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INTERNATIONAL APPLICATION PUBLISHED UNDER THE PATENT COOPERATION TREATY (PCT)

(51) International Patent Classification 5 :

C23C 14/34

A1

(11) International Publication Number:

WO 92/17621

(43) International Publication Date:

15 October 1992 (15.10.92)

(21) International Application Number: PCT/US92/00722

(22) International Filing Date: 29 January 1992 (29.01.92)

(30) Priority data:

681,866

4 April 1991 (04.04.91)

US

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Francisco, CA 94111-4156 (US).(81) Designated States: AT (European patent), BE (European
patent), CH (European patent), DE (European patent),
DK (European patent), ES (European patent), FR (Eu-
ropean patent), GB (European patent), GR (European
patent), IT (European patent), JP, KR, LU (European
patent), MC (European patent), NL (European patent),
SE (European patent).

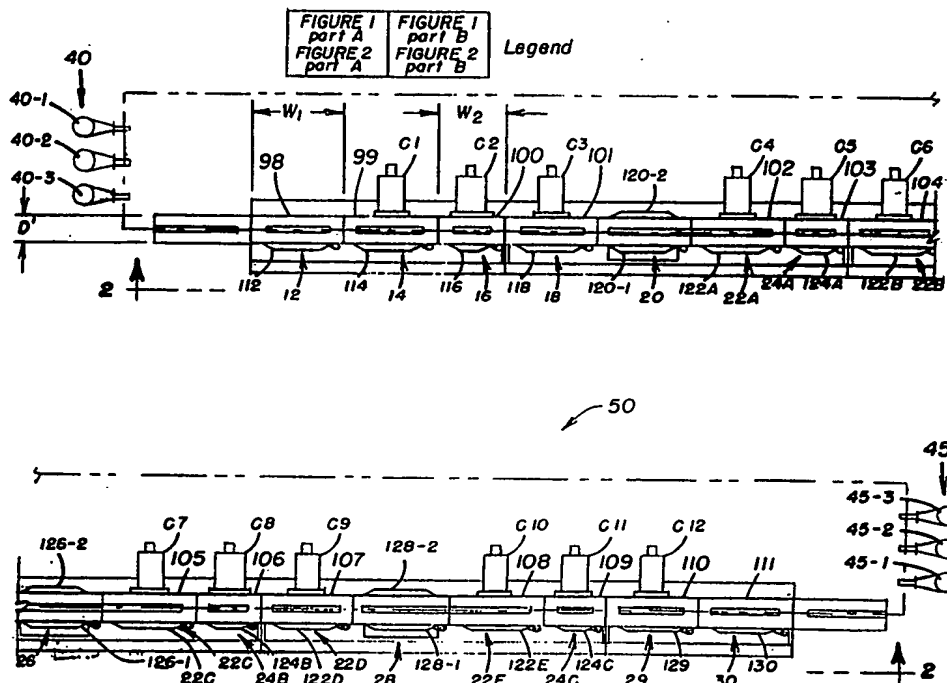
Published

With international search report.

(54) Title: APPARATUS AND METHOD FOR HIGH THROUGHPUT SPUTTERING

(57) Abstract

An apparatus provides a single or multi-layer coating to the surface of a plurality of substrates. The apparatus includes a plurality of buffer and sputtering chambers (12, 18, 20, 22A-E, 24A-C, 26 and 28-30), and an input end and an output end. The substrates are transported through said chambers (12, 18, 20, 22A-E, 24A-C, 26 and 28-30) at varying rates of speed. The apparatus may further include means for transporting a plurality of substrates through sputtering chambers (20, 26, 28) at variable velocities; means for reducing the ambient pressure within the sputtering chambers (20, 26, 28) to a vacuum level to enable sputtering operation; means for heating the substrates to a temperature conducive to sputtering coatings thereon providing a substantially uniform temperature profile over the surface of the substrates; and control means for providing control signals to and for receiving feedback input from, said sputtering chambers (20, 26, 28), means for transporting, means for reducing, and means for heating, the control means being programmable for allowing control over the means for sputtering, transporting, reducing and heating.



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APPARATUS AND METHOD FOR HIGH THROUGHPUT SPUTTERING

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10 BACKGROUND OF THE INVENTION1. Field of the Invention

The invention relates to an apparatus and method for depositing multilayer thin films in a magnetron sputtering process. More particularly, the invention
15 relates to an apparatus and method for depositing thin magnetic films for magnetic recording media in a high volume, electronically controlled, magnetron sputtering process, and to production of an improved magnetic recording disk product thereby.

20

2. Description of the Related Art

Sputtering is a well-known technique for depositing uniform thin films on a particular substrate. Sputtering is performed in an evacuated chamber using an
25 inert gas, typically argon, with one or more substrates remaining static during deposition, being rotated about

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the target (a "planetary" system) or being transported past the target (an "in-line" system).

Fundamentally, the technique involves bombarding the surface of a target material to be deposited as the film with electrostatically accelerated argon ions. Generally, electric fields are used to accelerate ions in the plasma gas, causing them to impinge on the target surface. As a result of momentum transfer, atoms and electrons are dislodged from the target surface in an area known as the erosion region. Target atoms deposit on the substrate, forming a film.

Typically, evacuation of the sputtering chamber is a two-stage process in order to avoid contaminant-circulating turbulence in the chamber. First, a throttled roughing stage slowly pumps down the chamber to a first pressure, such as about 50 microns. Then, high vacuum pumping occurs using turbo-, cryo- or diffusion pumps to evacuate the chamber to the highly evacuated base pressure (about 10^{-7} Torr) necessary to perform sputtering. Sputtering gas is subsequently provided in the evacuated chamber, backfilling to a pressure of about 2-10 microns.

The sputtering process is useful for depositing coatings from a plurality of target materials onto a variety of substrate materials, including glass, nickel-phosphorus plated aluminum disks, and ceramic materials. However, the relatively low sputtering rate achieved by the process solely relying on electrostatic forces (diode sputtering) may be impracticable for certain commercial applications where high volume processing is desired. Consequently, various magnet arrangements have been used to enhance the sputtering rate by trapping electrons close to the target surface, ionizing more argon, increasing the probability of impacting and

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dislodging target atoms and therefore the sputtering rate. In particular, an increased sputtering rate is achieved by manipulation of a magnetic field geometry in the region adjacent to the target surface.

5 Sputter deposition performed in this manner is generally referred to as magnetron sputtering.

10 The magnetic field geometry may be optimized by adjusting the polarity and position of individual magnets used to generate magnetic fields with the goal of using the magnetic field flux paths to enhance the sputtering rate. For example, U.S. Patent No. 4,166,018, issued August 28, 1989 to J. S. Chapin and assigned to Airco, Inc., describes a planar direct current (d.c.) magnetron sputtering apparatus which uses
15 a magnet configuration to generate arcuate magnetic flux paths (or lines) that confine the electrons and ions in a plasma region immediately adjacent to the target erosion region. A variety of magnet arrangements are suitable for this purpose, as long as one or more closed
20 loop paths of magnetic flux is parallel to the cathode surface, e.g., concentric ovals or circles.

25 The role of the magnetic field is to trap moving electrons near the target. The field generates a force on the electrons, inducing the electrons to take a spiral path about the magnetic field lines. Such a spiral path is longer than a path along the field lines, thereby increasing the chance of the electron ionizing a plasma gas atom, typically argon. In addition, field lines also reduce electron repulsion away from a
30 negatively biased target. As a result, a greater ion flux is created in the plasma region adjacent to the target with a correspondingly enhanced erosion of target atoms from an area which conforms to a shape approximating the inverse shape of the field lines.

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Thus, if the field above the target is configured in arcuate lines, the erosion region adjacent to the field lines conforms to a shallow track, leaving much of the target unavailable for sputtering.

5 Even lower target utilization is problematic for magnetic targets because magnetic field lines tend to be concentrated within, and just above, a magnetic target. With increasing erosion of the magnetic target during sputtering, the field strength above the erosion region
10 increases as more field lines 'leak' out from the target, trapping more electrons and further intensifying the plasma close to the erosion region. Consequently, the erosion region is limited to a narrow valley.

 In addition to achieving high film deposition rates,
15 sputtering offers the ability to tailor film properties to a considerable extent by making minor adjustments to process parameters. Of particular interest are processes yielding films with specific crystalline microstructures and magnetic properties. Consequently,
20 much research has been conducted on the effects of sputtering pressures, deposition temperature and maintenance of the evacuated environment to avoid contamination or degradation of the substrate surface before film deposition.

25 Alloys of cobalt, nickel and chromium deposited on a chromium underlayer (CoNiCr/Cr) are highly desirable as films for magnetic recording media such as disks utilized in Winchester-type hard disk drives. However, on disk substrates, in-line sputtering processes create
30 magnetic anisotropies which are manifested as signal waveform modulations and anomalies in the deposited films.

 Anisotropy in the direction of disk travel through such in-line processes is understood to be caused by

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crystalline growth perpendicular to the direction of disk travel as a result of the deposition of the obliquely incident flux of target atoms as the disk enters and exits a sputtering chamber. Since magnetic film properties depend on crystalline microstructure, such anisotropy in the chromium underlayer can disrupt the subsequent deposition of the magnetic CoNiCr layer in the preferred orientation. The preferred crystalline orientation for the chromium underlayer is with the closely packed, bcc {110} plane parallel to the film surface. This orientation for the chromium nucleating layer forces the 'C' axis of the hcp structure of the magnetic cobalt-alloy layer, i.e., the easy axis of magnetization, to be aligned in the film plane. Similarly, the orientation of the magnetic field generated in the sputtering process may induce an additional anisotropy which causes similar signal waveform modulations. See, Uchinami, et al., "Magnetic Anisotropies in Sputtered Thin Film Disks", IEEE Trans. Magn., Vol. MAG-23, No. 5, 3408-10, Sept. 1987, and Hill, et al., "Effects of Process Parameters on Low Frequency Modulation on Sputtered Disks for Longitudinal Recording", J. Vac Sci. Tech., Vol. A4, No. 3, 547-9, May 1986 (describing magnetic anisotropy phenomena).

Several approaches have been taken to eliminate the aforementioned waveform modulation problems while enhancing magnetic properties in the coating, especially coercivity. For instance, U.S. Patent No. 4,816,127, issued March 28, 1989 to A. Eltoukhy and assigned to Xidex Corp., describes one means for shielding the substrate to intercept the obliquely incident target atoms. In addition, Teng, et al., "Anisotropy-Induced Signal Waveform Modulation of DC Magnetron Sputtered Thin Films", IEEE Trans. Magn., Vol. MAG-22, 579-581,

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1986, and Simpson, et al., "Effect of Circumferential Texture on the Properties of Thin Film Rigid Recording Disks", IEEE Trans. Magn., Vol. MAG-23, No. 5, 3405-7, Sept. 1987, suggest texturizing the disk substrate surface prior to film deposition. In particular, the authors propose circumferential surface grooves to promote circumferentially oriented grain growth and thereby increase film coercivity.

Other approaches to tailoring film properties have focused on manipulating the crystalline microstructure by introducing other elements into the alloy composition. For example, Shiroishi, et al., "Read and Write Characteristics of Co-Alloy/Cr Thin Films for Longitudinal Recording", IEEE Trans. Magn., Vol. MAG-24, 2730-2, 1988, and U.S. Patent No. 4,652,499, issued March 24, 1987 to J. K. Howard and assigned to IBM, relate to the substitution of elements such as platinum (Pt), tantalum (Ta), and zirconium (Zr) into cobalt-chromium (CoCr) films to produce higher coercivity and higher corrosion resistance in magnetic recording films.

CoCr alloys with tantalum (CoCrTa) are particularly attractive films for magnetic recording media. For example, it is known in the prior art to produce CoCrTa films by planetary magnetron sputtering processes using individual cobalt, chromium and tantalum targets or using cobalt-chromium and tantalum targets.

Fisher, et al., "Magnetic Properties and Longitudinal Recording Performance of Corrosion Resistant Alloy Films", IEEE Trans. Magn., Vol. MAG 22, no. 5, 352-4, Sept. 1986, describe a study of the magnetic and corrosion resistance properties of sputtered CoCr alloy films. Substitution of 2 atomic percent (at.%) Ta for Cr in a Co-16 at.% Cr alloy (i.e., creating a Co-14 at.% Cr-2 at.% Ta alloy) was found to

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improve coercivity without increasing the saturation magnetization. In particular, a coercivity of 1400 Oe was induced in a 400 Å film. In addition, linear bit densities from 8386 flux reversals/cm to 1063 flux reversals/cm (21300 fci to 28100 fci) were achieved at -3 dB, with a signal-to-noise (SNR) ratio of 30 dB. Moreover, corrosion resistance of CoCr and CoCrTa films was improved relative to CoNi films.

U.S. Patent No. 4,940,548, issued on August 21, 1990 to Furusawa, et al., and assigned to Hitachi, Ltd., discloses the use of Ta to increase the coercivity and corrosion resistance of CoCr (and CoNi) alloys. CoCr alloys with 10 at.% Ta (and chromium content between 5 and 25 at.%) were sputtered onto multiple layers of chromium to produce magnetic films with low modulation even without texturing the substrate surface and highly desirable crystalline microstructure and magnetic anisotropy.

Development of a high throughput in-line system to produce sputtered CoCrTa films with enhanced magnetic and corrosion-resistance properties for the magnetic recording media industry has obvious economic advantages.

Linear recording density of magnetic films on media used in Winchester-type hard disk drives is known to be enhanced by decreasing the flying height of the magnetic recording head above the recording medium. With reduced flying height, there is an increased need to protect the magnetic film layer from wear. Magnetic films are also susceptible to corrosion from vapors present even at trace concentrations within the magnetic recording system. A variety of films have been employed as protective overlayers for magnetic films, including rhodium, carbon and inorganic nonmetallic carbides,

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nitrides and oxides, like silica or alumina. However, problems such as poor adhesion to the magnetic layer and inadequate wear resistance have limited the applicability of these films. U.S. Patent No. 4,503,125 issued on March 3, 1985 to Nelson, et al. and assigned to Xebec, Inc. describes a protective carbon overcoating for magnetic films where adhesion is enhanced by chemically bonding a sputtered layer of titanium between the magnetic layer and the carbon overcoating.

In the particular case of sputtered carbon, desirable film properties have been achieved by carefully controlling deposition parameters. For example, during the sputtering process, the amount of gas incorporated in the growing film depends on sputtering parameters like target composition, sputtering gas pressure and chamber geometry. U.S. Patent No. 4,839,244, issued on June 13, 1989 to Y. Tsukamoto and assigned to NEC Corp., describes a process for co-sputtering a protective graphite fluoride overlayer with an inorganic nonmetallic compound in a gaseous atmosphere which includes fluorine gas. U.S. Patent No. 4,891,114 issued on January 1, 1990 to Hitzfeld, et al., and assigned to BASF Aktiengesellschaft of Germany, relates to a d. c. magnetron sputtering process for an amorphous carbon protective layer using a graphitic carbon target.

As the wear-resistant layer for magnetic recording media, it is desirable that the carbon overlayer have a microcrystalline structure corresponding to high hardness. In other words, it is desirable during sputtering to minimize graphitization of carbon which softens amorphous carbon films. One means employed to moderate graphitization of sputtered carbon films is by incorporating hydrogen into the film. Such

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incorporation may be accomplished by sputtering in an argon atmosphere mixed with hydrogen or a hydrogen-containing gas, such as methane or other hydrocarbons.

5 Magnetron sputtering processes have been developed which have been somewhat successful in achieving high throughput. For example, U.S. Patent Nos. 4,735,840 and 4,894,133 issued to Hedgcoth on April 5, 1988 and April 16, 1990, respectively, describe a high volume planar d. c. magnetron in-line sputtering apparatus 10 which forms multilayer magnetic recording films on disks for use in Winchester-type hard disk technology. The apparatus includes several consecutive regions for sputtering individual layers within a single sputtering chamber through which preheated disk substrates mounted 15 on a pallet or other vertical carrier proceed at velocities up to about 10 mm/sec (1.97 ft/min), though averaging only about 3 mm/sec (0.6 ft/min). The first sputtering region deposits chromium (1,000 to 5,000 Å) on a circumferentially textured disk substrate. The 20 next region deposits a layer (200 to 1,500 Å) of a magnetic alloy such as CoNi. Finally, a protective layer (200 to 800 Å) of a wear- and corrosion-resistant material such as amorphous carbon is deposited.

The apparatus is evacuated by mechanical and cryo 25 pumps to a base pressure about 2×10^{-7} Torr. Sputtering is performed at a relatively high argon pressure between 2 and 4×10^{-2} Torr (20 to 40 microns) to eliminate anisotropy due to obliquely incident flux.

In optimizing a sputtering process to achieve high 30 throughput, consideration should be given to other time-influenced aspects of the process apart from the sputtering rate. For example, substrate heating is typically accomplished with heaters requiring an extended dwell time to warm substrates to a desired

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equilibrium temperature. In addition, substrate transport speeds through the sputtering apparatus have been limited with respect to mechanisms using traditional bottom drive, gear/belt-driven transport systems. Such bottom drive systems generally have intermeshing gears and may be practically incapable of proceeding faster than a particular rate due to rough section-to-section transitions which may dislodge substrates from the carrier and/or create particulate matter from gear wear which contaminates the disks prior to or during the sputtering process. Thus, overall process throughput would be further enhanced by the employment of heating and transport elements which require minimal time to perform these functions.

Generally, prior art sputtering devices utilize relatively unsophisticated means for controlling the sputtering processes described therein. Such control systems may comprise standard optical or electrical metering monitored by a system operator, with direct electrical or electro-mechanical switching of components utilized in the system by the system operator. Such systems have been adequately successful for limited throughput of sputtered substrates. However, a more comprehensive system is required for higher throughput sputtering operations. Specifically, a control system is required which provides to the operator an extensive amount of information concerning the ongoing process through a relatively user-friendly environment. In addition, the control system must adequately automate functions both in series and in parallel where necessary to control every aspect of the sputtering system. Further, it is desirable to include within such a control system the capability to preset a whole series of operating parameters to facilitate rapid set-up of

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the system for processes employing myriad sputtering conditions.

SUMMARY OF THE INVENTION

5 Thus, an object of the present invention is to provide a high throughput sputtering process and apparatus.

10 A further object of the present invention is to provide a control system for the apparatus and process which continuously monitors and facilitates alteration of film deposition process parameters.

 A further object of the present invention is to provide a high throughput sputtering apparatus with a centralized electronic control system.

15 An additional object of this invention is to provide the above objects in a means by which sputtering is achieved in a highly efficient, contaminant-free environment.

20 An additional object of this invention is to provide a highly versatile, contaminant-free means for transporting substrates through the apparatus and process.

25 A further object of this invention is to transport substrates through the sputtering apparatus by means of an overhead, gearless transport mechanism.

 A further object of this invention is to provide a transport mechanism for carrying a plurality of substrates, each at a user-defined, variable speed.

30 A further object of this invention is to maintain a contaminant-free environment within the sputtering apparatus by means of a high speed, high capacity vacuum pump system.

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A further object of this invention is to provide a magnetron design allowing efficient erosion of target material during the sputtering process.

5 A further object of this invention is to provide a high throughput sputtering apparatus which achieves and maintains a uniform substrate surface temperature profile before film deposition.

10 A further object of this invention is to provide a highly isotropic film by minimizing deposition by target atoms impinging on the substrate surface at high angles of incidence.

15 A further object of this invention is to provide high throughput sputtering apparatus which minimizes oxidation of the chromium underlayer before magnetic film deposition.

An additional object of the present invention is to provide high quality thin magnetic films on magnetic recording media with superior magnetic recording properties.

20 A further object of this invention is to provide high quality thin cobalt-chromium-tantalum (CoCrTa) films with superior magnetic recording properties.

25 A further object of this invention is to provide high quality sputtered thin magnetic films circumferentially oriented along the easy magnetic axis.

A further object of this invention is to provide high throughput sputtering apparatus for high quality thin carbon films with superior wear, hardness, corrosion and elastic properties.

30 A further object of this invention is to provide a method for depositing wear-resistant carbon films comprising sputtering in the presence of a hydrogen-containing gas.

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A further object of this invention is to provide an improved method for sputtering carbon films using either an electrically biased or grounded pallet.

These and other objects of the invention are
5 accomplished in a high throughput sputtering apparatus and process capable of producing sputtered substrates at a rate of up to five times greater than the prior art. An apparatus in accordance with the present invention provides a single or multi-layer coating to the surface
10 of a plurality of substrates. Said apparatus includes a plurality of buffer and sputtering chambers, and an input end and an output end, wherein said substrates are transported through said chambers of said apparatus at varying rates of speed such that the rate of speed of a
15 pallet from said input end to said output end is a constant for each of said plurality of pallets. A high throughput sputtering apparatus having a plurality of integrally matched components in accordance with the present invention may comprise means for sputtering a
20 multi-layer coating onto a plurality of substrates, said means for sputtering including a series of sputtering chambers each having relative isolation from adjacent chambers to reduce cross contamination between the coating components being sputtered onto substrates
25 therein, said sputtering chambers being isolated from ambient atmospheric conditions; means for transporting said plurality of substrates through said means for sputtering at variable velocities; means for reducing the ambient pressure within said means for sputtering to
30 a vacuum level within a pressure range sufficient to enable sputtering operation; means for heating said plurality of substrates to a temperature conducive to sputtering said multi-layer coatings thereon, said means for heating providing a substantially uniform

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temperature profile over the surface of said substrate; and control means for providing control signals to and for receiving feedback input from, said means for sputtering, means for transporting, means for reducing and means for heating, said control means being programmable for allowing control over said means for sputtering, means for transporting, means for reducing and means for heating.

A process in accordance the present invention includes: providing substrates to be sputtered; creating an environment about said substrates, said environment having a pressure within a pressure range which would enable sputtering operations; providing a gas into said environment in a plasma state and within said pressure range to carry out sputtering operations; transporting substrates at varying velocities through said environment a sequence of sputtering steps within said environment and along a return path external to said environment simultaneously introducing the substrates into said environment without substantially disrupting said pressure of said environment, providing rapid and uniform heating of said substrates to optimize film integrity during sputtering steps, and sputtering said substrates to provide successive layers of thin films on the substrates; and, removing the sputtered substrates without contaminating said environment.

BRIEF DESCRIPTION OF THE DRAWINGS

The invention will be better understood by reference to the figures of the drawings wherein like numbers denote like parts throughout and wherein:

Figure 1 is a system plan view of the sputtering apparatus of the present invention.

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Figure 2 is a cross sectional view along line 2-2 of the sputtering apparatus of the present invention as shown in Figure 1.

5 Figure 3 is a plan view of the sputtering apparatus of the present invention illustrating the physical relationship of the power supply and pumping subsystem components.

Figure 4 is an overview block diagram of the sputtering process of the present invention.

10 Figure 5 is a simplified perspective view of the means for texturing disk substrates used in the process of the present invention.

Figure 6 is a cross sectional view along line 6 - 6 of the cam wheel utilized in the means for texturing shown in Figure 5.

15 Figure 7 is a sectional magnified view of the texturing of a disk surface provided by the means for texturing disclosed in Figure 5.

Figure 8 is a surface view of one embodiment of a pallet for carrying disks through the sputtering apparatus of the present invention.

Figure 9 is a partial, enlarged view of the pallet of Figure 8.

20 Figure 10 is a partial, enlarged view of one region for carrying a disk in the pallet of Figure 9.

Figure 11 is a cross sectional view along 11 - 11 of the disk carrying region shown in Figure 10.

Figure 12 is an overview diagram of the pumping system used with the apparatus of the present invention.

30 Figure 13 is a side, partial cutaway view of a sputtering chamber utilized in the apparatus of the present invention.

Figure 14 is an assembled cross sectional view of the substrate transport mechanism, sputtering

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shields, and pallet viewed along line 14 - 14 of Figure 13.

Figure 15 is a cross sectional view of the main (or "dwell") heating lamp assembly and chamber.

5 Figure 16 is a view of the main heating lamp assembly along line 16 -16 in Figure 15.

Figure 17 is a view of the main heating lamp mounting tray and cooling lines along line 17 - 17 in Figure 15.

10 Figure 18 is a cross sectional view of the secondary (or "passby") heating lamp and chamber assembly.

Figure 19 is a view of the heating lamp assembly along line 19 - 19 in Figure 18.

15 Figure 20 is a view of the secondary heating lamp, mounting tray and cooling lines along line 20 - 20 in Figure 18.

20 Figure 21 is a perspective, partial view of a heat reflecting panel, pallet, and substrate transport system utilized in the apparatus present invention.

Figure 22 is a perspective, exploded view of a portion of a pallet, substrate transport mechanism, sputtering shield, and cathode assembly utilized in the sputtering apparatus of the present invention.

25 Figure 23 is a top view of the sputtering chamber shown in Figure 13.

Figure 24 is a cross-sectional, side view along line 24 - 24 of Figure 23.

30 Figure 25 is a partial perspective view of a first surface of the cathode portion of the magnetron of the present invention.

Figure 26 is a perspective view of a second surface of the cathode of the magnetron of the present

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invention, including cooling line inputs and magnet channels of the cathode.

Figure 27A is a cross-sectional, assembled view of a first embodiment of the magnet configuration in the cathode for a nonmagnetic target of the present invention along line 27 - 27 of Figure 25.

Figure 27B is a cross-sectional, assembled views of a second embodiment of the magnet configuration in the cathode for magnetic target of the present invention along line 27 - 27 of Figure 25.

Figure 28 is a cross sectional view of the multi-layer sputtered thin film created by the process of the present invention.

Figure 29 is a block diagram of the electronic control system of the present invention.

Figure 30 is a block flow chart of functional aspects of the software utilized in the process controller(s) of the present invention.

Figure 31 is a flow chart of the automated cryogenic pump regeneration process of the present invention.

Figures 32A through 32D comprise a single logical flow diagram outlining the software logic controlling the motor assemblies, load lock and exit lock pumping, and heater power during the automatic substrate run mode of the software utilized in the electronic control system of the present invention.

DESCRIPTION OF THE PREFERRED EMBODIMENT

30 A. Introduction

Described herein is an apparatus and method for applying multilayer thin films to a substrate. The apparatus of the present invention is capable of applying the multilayer coatings to any given substrate

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within a time frame of approximately five minutes. The apparatus and process may provide production throughputs on the order of at least five times greater than those of prior art multi-layer coating processes.

5 Other advantages of the sputtering apparatus and method for high throughput sputtering include: flexibility with respect to the composition of the multilayer films applied and the types of substrates to which they are applied; easily interchanged coating
10 components; a novel means for heating substrates; a novel sputtering magnetron design; a variable speed, overhead, noncontaminating substrate transportation system; and a comprehensive, centralized, programmable electronic means for controlling the apparatus and
15 process. In addition, when the process and apparatus are used for providing magnetic coatings for substrates, such as disks, to be utilized in hard disk drives using Winchester-type technology, also disclosed herein are: a unique disk texturing method for improving the disk's
20 magnetic recording properties, and a novel disk carrier (or pallet) design which contributes to uniform substrate heating characteristics in a large, single, high capacity pallet.

25 The high throughput process and apparatus of the present invention accomplishes the objectives of the invention and provides the above advantages by providing a comprehensive in-line sputtering system utilizing matched component elements to process multiple large
30 single sheet or pallet transported discrete substrates in a continuous, variable speed, sputtering process wherein each substrate has a start-to-finish process time which is relatively constant. Such an apparatus and method can process up to 3,000 95mm disk substrates, and 5,300 65mm disk substrates, per hour. In the disk

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drive industry where cost savings per disk on the order of a few cents are a distinct advantage, the system manufactures 95mm disk substrates at a cost of \$8.00 per disk as opposed to \$12.00 per disk for other sputtering apparatus. Crucial to this process and apparatus are matching and optimizing such elements as disk preparation, including texturing and cleaning, provision of a sputtering environment with a sputtering apparatus, through an optimal vacuum pump system, transporting disk substrates through the sputtering environment in a high volume, high speed, contaminant-free manner without disturbing the sputtering environment, heating the substrates within the environment to optimal thermal levels for sputtering, and sputtering the substrates through a series of substantially isolated, non-crosscontaminating sputtering steps.

In general, application of multilayer films to a substrate involves two basic steps: preparation of the substrate and film deposition. Figure 4 represents a general overview of the process for applying thin films to a disk substrate according to the present invention. In particular, Figure 4 outlines the process steps for providing a single or multilayer film on a substrate, for example, a nickel-phosphorus plated aluminum disk for use in Winchester-type hard disk drives. It will be recognized by those skilled in the art that the steps outlined in Figure 4 may be modified, as required, depending on the particular type of substrate to be coated or thin film to be applied.

Substrate preparation process 410 of Figure 4 includes: kitting process 412; disk texturing process 414, disk precleaning 416; water rinse 418; ultrasonic cleaning with caustic cleaner 420; a sponge scrubbing in water 422; an ultrasonic cleaning in hot deionized water

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424; scrubbing and deionizing water spray rinse 426; overflow deionized water rinse 428; ultrasonic cleaning of the disks with warm FREON TES 430; a cool FREON TES rinse 432; and vapor displacement drying in warm FREON TES 434. Each of the aforementioned steps outlined in Figure 4 is discussed in further detail in Section C of the specification.

Subsequent to the substrate preparation process 410, the clean, dry disk substrates may be provided to pallet loading process 450, wherein the disk substrates are provided to a substrate carrier which transports the disk substrates through coating process 460.

In coating process 460, disk substrates are provided to a coating apparatus, such as sputtering apparatus 10 shown in Figures 1 and 2, for provision of single or multilayer film thereon. The steps involved in coating process 460, such as in, for example, sputtering apparatus 10 of the present invention, involve: a system evacuation process 472 wherein specific chambers of the sputtering system are evacuated to a pressure of approximately 10^{-7} Torr and backfilled with a suitable sputtering gas, such as argon; a substrate heating process 476, wherein the substrates are raised to a temperature conducive to optimal film deposition; and a sputtering process 478 wherein the films are deposited on the substrates. Subsequently, the substrates are provided to an unload process 480. A process for transporting pallets 474 provides means for transporting the substrates through the above processes.

Each of the aforementioned steps with respect to applying the multilayer films to the substrates is discussed below in detail in separate sections of this specification.

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B. Sputtering Apparatus Overview

Sputtering apparatus 10, used to apply a single or multilayer film to one or more substrates, will be discussed generally with reference to Figures 1A, 1B, 2A, 2B, and 3. Sputtering apparatus 10 provides a high throughput, in-line, magnetron sputtering process which allows reduced manufacturing costs per substrate by performing the coating sequence in a high volume manner. As will be discussed in detail below, single or multilayer film can be applied to a single side, or both sides, individually or simultaneously, of a single large sheet substrate, or to discrete substrates, such as disks mounted in a rack, pallet or other substrate carrier.

Generally, substrates are provided through multiple sputtering chambers 20, 26, 28 in apparatus 10 at a rate of speed, such as 3-6 feet/minute, and through heater chambers 14, 16 and buffer chambers 12, 18, 22A-E, 24A-24C, 29 and 30, at a second rate of speed, such as 12 feet/minute. Through carefully matched elements, each of the substrates has a constant speed through apparatus 10.

Sputtering apparatus 10 includes seventeen (17) chamber modules 12-30 generally comprised of two basic types. A first type is configured for use as lock modules (12, 30), deposition process modules (20, 26, 28) or dwell modules (14, 18, 22A-22D and 29). A second type of module is configured for use as high vacuum buffer modules (16, 24A-24C) to provide process separation between deposition modules as discussed below.

Also shown in Figures 1 and 2 is substrate carrier return path 50 of the transport system of the present invention. Preferably, return path 50 is provided to

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allow an ample number of substrate carriers to return from exit lock 30 for reuse in sputtering apparatus 10 in a continuous process, thereby reducing production delays and increasing overall process production speed.

5 In addition, Figures 1 and 2 illustrate robotic pallet loading station 40 and robotic pallet unloading station 45, arranged along the transport system return path 50, for automatic loading and unloading, respectively, of the disk substrates into racks or pallets. As discussed

10 in detail below, the substrate transport system utilizes a plurality of individual transport beam platforms, each including one or more optical or proximity position sensors, to move substrates through sputtering apparatus 10 and along return path 50, and to monitor the position

15 of each substrate carrier within the transport system. Transfer speeds of the substrate carriers throughout the transport system may be adjustably varied from 0 to 24 ft/min. It should be noted that the upper limit of substrate carrier transport speed is constrained by the

20 process limits of sputtering apparatus 10. Each individual drive stage (2200, discussed in Section F of this specification) is identical and thus has identical upper and lower speed limits.

Twelve (12) pneumatically operated doors D1-D12 are

25 placed between specific chamber modules 12-30 of sputtering apparatus 10. Doors D1-D12 are located as generally represented in Figure 12 and are positioned as follows: door D1 isolates chamber 12 from the ambient environment; door D2 isolates load lock chamber

30 12 from main ("dwell") heating chamber 14; door D3 isolates main heating chamber 14 from first buffer-passby heating chamber 16; door D4 isolates buffer chamber 16 from first dwell chamber 18; doors D5-D6 isolate second buffer chamber 24A from third dwell

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chamber 22B; doors D7-D8 isolate third buffer chamber 24B from fifth dwell chamber 22D; doors D9-D10 isolate fourth buffer chamber 24C from exit buffer 29; door D11 isolates exit buffer chamber 29 from exit lock chamber 30; and door D12 isolates exit lock chamber 30 from the ambient environment.

With reference to Figures 1-3 and 12, the general arrangement of chamber modules 12-30 will be hereinafter discussed. Load lock chamber 12 is essentially an isolation chamber between the ambient environment and chambers 14-29 of sputtering apparatus 10. Load lock chamber 12 is repeatedly evacuated between a pressure of approximately 50 mTorr and vented to ambient atmospheric conditions. Generally, sputtering within apparatus 10 takes place in an evacuated environment and chambers 16-29 are evacuated to the pressure of approximately 10^{-7} Torr, before argon gas is allowed to flow into the chambers to achieve a suitable sputtering pressure. Load lock chamber 12 is constructed of one-inch thick type 304 stainless steel and has a width W_1 of approximately 39 inches, length L_1 of approximately 49 inches, and a depth D_1 of approximately 12 inches as measured at the exterior walls of the chamber. The use of electropolished stainless steel in load lock chamber 12 and all other chambers in apparatus 10 minimizes particulate generation from scratches and other surface imperfections. Chambers 14, 18, 20, 22A-22D, 24A-24C, 26 and 28-30 have roughly the same dimensions. The internal volume of load lock chamber 12 is reduced to approximately three cubic feet by the installation therein of volume-displacing solid aluminum blocks bolted to the chamber door and rear wall (not shown) to facilitate faster evacuation times. Pump-down of load

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lock chamber 12, and sputtering apparatus 10 in general, is discussed below in Section F of the specification.

After door D1 is pneumatically operated to allow a single large substrate or pallet to enter load lock chamber 12 at the initiation of processing by sputtering apparatus 10, load lock chamber 12 will be evacuated to a pressure of 50 microns (50 mTorr). Chambers 16-29 will have been evacuated to a base pressure of about 10^{-7} Torr and then backfilled with argon to the sputtering pressure (approximately 9-12 mTorr) prior to the entrance of a substrate into load lock chamber 12. Chamber 14 will have been evacuated previously to a pressure of approximately 10^{-5} - 10^{-7} Torr. Load lock chamber 12 is thus mechanically evacuated and pressurized at a level intermediate to that of chambers 14-29, and external ambient pressures, to provide isolation for the downstream sputtering processes occurring in chambers 14-29.

Dwell heating chamber 14 serves two functions: it acts as an entrance buffer between load lock chamber 12 and the internal sputtering environment in chambers 16-29; and it serves as a heating chamber for increasing the substrate temperature to optimize film deposition. Chamber 14 includes eight banks of quartz lamp heating elements, four banks mounted to outer door 114 and four banks mounted opposite thereof on rear chamber wall 99. Door D2, separating load lock chamber 12 and dwell heating chamber 14, is a high vacuum slit valve. Details of the heating banks located in dwell heating chamber 14 are discussed in Section H of this specification.

During processing of a substrate, dwell heating chamber 14 is pumped to a pressure of approximately

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10⁻⁵ - 10⁻⁷ Torr before the substrate present in load lock chamber 12 is allowed to pass into dwell heating chamber 14. A pressure of 10⁻⁵ - 10⁻⁷ Torr helps eliminate the effects of outgassing from the substrate in dwell heating chamber 14. Subsequently argon backfilling is provided to raise the pressure to approximately 9-12 mTorr, equalizing the environment in dwell heating chamber 14 with that in chambers 16-29. The substrate may thereafter remain in dwell heating chamber 14 for the duration of time necessary for the exposure of the substrate to the lamps to have its desired effect.

First buffer-passby heating chamber 16 is a chamber module of the second type having a width W_2 of approximately 26 inches by a height H' of approximately 49 inches by a depth D' of approximately 12 inches. In general, buffer chambers 16 and 24A-C are positioned between dwell chambers 18A and 22A-D to separate the ongoing sputtering processes within apparatus 10, thereby reducing cross-contamination of coating components.

First buffer-passby heating chamber 16 includes a heating assembly comprising ten banks of quartz lamp heating elements, five mounted to outer door 116 and five to the rear chamber 100 wall opposite thereof. Passby heating chamber 16 is designed to insure uniform substrate temperature prior to film deposition. The structure of the passby heating assembly is discussed in detail in Section H of this specification.

Three coating modules -- chromium deposition chamber 20, magnetic deposition chamber 26, and carbon deposition chamber 28 -- having dimensions roughly equal to those of load lock chamber 12 and constructed of type 304 electropolished stainless steel, may be utilized to sputter single or multilayer films on a substrate

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passing through apparatus 10. Four pairs of d. c. magnetron sputtering cathodes are mounted, four magnetrons per door, on doors 120-1, 120-2, 126-1, 126-2, 128-1, and 128-2 on both sides of each chamber 20, 26, and 28, respectively. Target materials are mounted to cathodes 2222-2225. Anodes 2338, gas manifolds 2323, and shielding 2230, 2236, 2238 and 2240 are also attached to outer doors 120-1, 120-2, 126-1, 126-2 and 128-1, 128-2. Mounting these components to the doors facilitates target changes and chamber maintenance. Further, conduits (not shown) for power, cooling, and process gases are provided in outer doors 120, 126, 128. Feedthrough conduits are also provided in doors 112, 114, 116, 118, 122A-122E, 124A-124C, 129, and 130 to allow for modification of the sputtering apparatus 10. Details of deposition chambers 20, 26 and 28 are provided in Section I of this specification.

Dwell chambers 18 and 22A-22E are manufactured to have the same dimensions as load lock chamber 12 and provide separation between the buffer modules and the deposition chambers. Dwell modules 18 and 22A-22E allow for substrate transport system runout, if necessary, during multiple substrate processing in sputtering apparatus 10. If desired, additional heating assemblies may be provided in any or all of dwell modules 22A-22E.

Exit buffer module 29 is essentially identical to dwell heating chamber 14, without the dwell heating assembly hardware. Exit buffer module 29 provides a buffer area to facilitate removal of pallets or substrates from sputtering apparatus 10 to exit lock chamber 30 and further isolates the sputtering process from the external environment.

Exit lock chamber 30 is essentially identical to load lock chamber 12 and operates in reverse pumping

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order, allowing pallets or substrates to be transferred from the evacuated environment of sputtering apparatus 10, to the ambient external environment.

Optimally, sputtering apparatus 10 can simultaneously process up to seven large single sheet substrates or pallets carrying smaller substrates, such as disks. When seven such substrates are simultaneously processed in sputtering apparatus 10, one such substrate is positioned in each of seven chambers, for example, as follows: load lock chamber 12; dwell heating chamber 14; chromium deposition chamber 20; magnetic deposition chamber 26; carbon deposition chamber 28; exit buffer chamber 29; and exit lock chamber 30. The sheer dimensions of sputtering apparatus 10 allow for a plurality of large single sheet substrates, and a plurality of high capacity discrete substrate carrying pallets, or both, to be simultaneously processed. The problems attending the development of such a large scale, high throughput sputtering apparatus, and the solutions adopted, are discussed herein.

Chambers 12-30 are mounted on steel assembly rack 150. Rack 150 includes channels 55 which preferably are used to mount components used with sputtering apparatus 10, such as those used in the electronic control system. It will be understood by those skilled in the art that any suitable arrangement for mounting chambers 12-30 may be made within contemplation of the present invention.

C. Substrate Preparation

Various materials in the form of large single sheet or discrete substrates may be coated in sputtering apparatus 10. Suitable substrates include polished nickel-phosphorus plated aluminum disks, ceramic disks (available from Kyocera Industrial Ceramics Corporation,

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Los Angeles, California, or Corning Glass Corporation, Corning, New York), glass substrates (available from Pilkington Corporation Microelectronics, Ltd., Toledo, Ohio, Nederlandse Philips Bedrijven B.V., The Netherlands, or Glaverbel Corporation Data Storage Glass Products, Belgium), or carbon substrates or graphite substrates (Kao Corporation of Japan). The process and apparatus disclosed herein is discussed with regard to preparation and sputtering of polished nickel-phosphorus plated aluminum substrates, such as disks suitable for use in Winchester-type hard disk drives. As will be understood by those skilled in the art, the system is readily adaptable for use with other types of single sheet or discrete substrates as discussed above.

15

1. Kitting

In general, polished nickel-phosphorus plated aluminum disks or similar substrates utilized in the manufacture of magnetic recording media for Winchester-type hard disk drives, such as those available from Mitsubishi Corporation or Seagate Corporation, are shipped to magnetic media manufacturers in standard ribbed or slotted shipping cassettes, 25 substrates per cassette. Transfer of the substrates from the shipping cassettes to process cassettes, used in processing the disks through texturing process 414 and up through pre-cleaning process 416, is known as kitting. Kitting must occur in a class 10,000 clean room environment and is generally performed manually.

30

2. Texturing

It is well known in the art that circumferential texturing or abrading of a substrate surface can cause the hcp "C" axis of a magnetic cobalt-alloy film to

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orient in a circumferential direction, and thereby supply a more intense and uniform read/back signal to a flying read/write head in a Winchester-type hard disk drive. Texturing the disk substrate also affects the
5 glide properties of the read/write head. Obviously, the texture of the disk surface also provides a limit to the minimum flying height of the read/write head. Texturing of the substrate also prevents stiction which may result should the head land on a smooth, planar area
10 of the disk, thereby resulting in a job-blocking effect, rendering it almost impossible to remove the stuck read/write head from the disk surface, and rendering a disk drive entirely inoperable.

Texturing generally takes place in a class 1,000
15 clean room and, as previously discussed, any number of well-known methods may be used.

In the preparation of substrates to be coated within sputtering apparatus 10, a plurality of texturing machines, such as Exclusive Design Company's EDC Model
20 C texturing machine, (EDC, 914 South Clairmont, San Mateo, California 94402) are used. A novel modification to each EDC texturing machine provides a unique, diamond-shaped texturing effect. A portion of a disk surface having such texturing is illustrated in Figure
25 7.

With reference to Figures 5 through 7, texturing process 414 will be hereinafter described in relation to the texturing of discrete disk substrates 510
suitable for use in sputtering apparatus 10.

30 Figure 5 is a general disclosure of the texturing portion 500 of texturing machine M.

Generally, texturing of disk substrate 510 is performed using two loops of fixed abrasive tape 515 which are stretched about rubber rollers 520-1, 520-2.

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Abrasive tape 515 for each roller 520 is provided by two reels, one supply reel and one take-up reel (not shown), in a single feed direction with a portion of abrasive tape 515 looped about rollers 520. Abrasive tape 515 makes only one transition from the supply reel to the take-up reel during a normal texturing cycle. Rollers 520-1 and 520-2 rotate about spindles 522-1 and 522-2, respectively, mounted to oscillation arm 525 of machine M.

A second set of rubber rollers 530-1, 530-2, and associated supply and take-up reels, (not shown), allow for mounting a fine cloth tape 535 to remove excess particulate matter generated by abrasive tape 515 as disk 510 is texturized. Like abrasive tape 515, cloth tape 535 is used only once from supply reel to take-up reel.

Cam assembly 550 causes arm 525, rollers 520-1, 520-2, and abrasive tape 515 to oscillate in the direction of axis X. Cam assembly 550 includes cam wheel 600 fixed by two set screws (not shown) to spindle 560 which is rotated in a counterclockwise direction about axis Y_1 by machine M. Cam wheel 600 contacts first and second rollers 570, 575, rotatably mounted to support members 572, 574, respectively, to translate the motion defined by rotation of cam wheels 600 to oscillation arm 525.

In operation, disk substrate 510 is mounted on spindle 540 of machine M and rotated in a clockwise direction about axis Y_2 passing through the center of spindle 540. To mount a disk substrate 510, machine M causes rollers 520 and 530 to linearly separate in opposing directions along paths parallel axes $Y_{1,2}$ allowing disk substrate 510 to be inserted and removed by an automatic loading apparatus (not shown) onto spindle 540. Disk substrate 510 is then rotated about

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axis Y_2 in a clockwise direction. Simultaneously thereto, abrasive tape 515 and cloth tape 535 are rotated about rollers 520-1, 520-2 and 530-1, 530-2, respectively, such that rollers 520-2 and roller 530-1 rotate in a clockwise direction, and rollers 520-1 and 530-2 rotate in a counterclockwise direction. Thus, opposing rollers 520-1, 520-2 and 530-1, 530-2 rotate in directions opposite to each other and in a direction opposing the direction of rotation of disk substrate 510, to provide optimal disk texturing and cleaning. As rollers 520 and 530 are rotated, machine M simultaneously rotates spindle 560, and hence cam wheel 600, causing rollers 520 to oscillate about axis X.

As a result of the unique shape cam wheel 600, discussed with reference with Figures 6A-6B, a novel cross-hatched type texturing 700 results. With reference to Figure 7, texturing process 414, discussed above, generally forms diamond-shaped areas 750 defined by a plurality of crossing texture lines 740 provided to a depth of 60 μm . When lines 740 intersect, they define a plurality of angles θ in a range of approximately 6 to 10 degrees. It has been determined that an angle greater than 10 degrees, while providing generally excellent properties of low dynamic friction and low stiction, results in problems with the magnetic recording properties such as bit dropouts or shifts in areas adjacent to intersecting texturing lines. To compensate, a higher coercivity alloy is required on the substrate. These problems are within acceptable levels when angle θ is within a range of 4'-10'. An angle of 6 degrees or less improves the magnetic recording capability of the record media, but sacrifices in stiction and running friction properties of the disk are made for θ less than 6 degrees. Preferably, when

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rotation Y_1 of cam wheel 600 is approximately 6 Hertz, angles θ of approximately 6° will result.

The structure of cam wheel 600 is detailed in Figure 6A and 6B. Figure 6A shows cross-section cam wheel 600 along line 6-6 in Figure 5. Cam wheel 600 has a shape wherein the radial distance R between axis Y_1 and outer edge 710, is at a minimum distance R_1 at reference point 720, and at a maximum distance R_2 at point 730, 180° opposite point 720.

Currently, two types of cams are used in the machine M for texturing disk substrates 510, depending on the size of disk substrate 510. In one embodiment, the distance R_2 equals one inch and distance $R_1 = .760$ inch. Figure 6B illustrates the distance of all points along outer edge 710 from axis Y_1 . As can be seen therein, radial distance R from outer diameter 710 to axis Y_1 is evenly sloped from the point 720 to point 730, of 180° opposite from point 720. Assuming a line from axis Y_1 to point 720 is used as a reference, the distance of all points along outer edge 710 from axis Y_1 in one embodiment is as follows: the distance R_1 at point 720 = .756 inch, the distance at 60° and 300° angles from point 720 = .840 inch, the distance at 120° and 240° from point 720 = .920 inch, and the distance R_2 at 180° from point 720 (point 730) = 1.00 inches.

In the above embodiment, cam wheel 600 may be manufactured by beginning with a completely circular cam wheel and removing outer edge 720 of cam wheel 600 in equal linear to rotational increments. For example, at point 730, no material is removed, moving 3 degrees to the left or right, the cutting device is adjusted to move in a distance toward axis Y_1 of approximately .004 inch, and is thereafter moved .004 inch closer to axis Y_1 for every 3° of rotational movement about axis

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Y₁. In this manner, one embodiment of cam wheel 600 may be manufactured; those skilled in the art will recognize that various sizes and types of cam wheels may be manufactured in like manner for various sizes of disk substrates 510.

3. Disk Cleaning

Following texturing, the disk surface is cleaned to facilitate uniform film deposition, for example, by performing the following steps, represented as stage 416 in Figure 4.

During precleaning process 416, each disk surface is rubbed with a polyurethane soap pad. In an automated process, textured disk substrates are removed from process cassettes and placed in a precleaning machine such as the Model MDS1, commercially available from Speed Fam Corporation of Tempe, Arizona. In the Speed Fam machine described above, a plurality of disk substrates is arranged about a large pad assembly in a cylindrical tank, thereby allowing rapid disk cleaning (up to 350 95-mm disks per hour) by performing precleaning process 416 on a number of disk substrates simultaneously.

An additional preparation step involves taking disk substrates through a multi-staged cleaning process 435. This process is illustrated generally in Figure 4 as stages 418 through 434. Each stage, for example, may represent a separate tank process wherein all tanks are connected with a conveyor system. In addition, transfer between individual stages may be performed by robots.

Specifically, disk substrates 510 are rinsed in water at stage 418, followed by several ultrasonic cleaning stages (420, 424 and 430) and sponge scrubbing stages (422 and 426). The multistage cleaning process

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435 processing stages include water rinse 418; ultrasonic cleaning with caustic cleaner 420; a sponge scrubbing in water 422; an ultrasonic cleaning in hot deionized water 424; ultrafiltered deionized water spray
5 rinse 426; overflow deionized water rinse 428; ultrasonic cleaning of disk substrates with warm FREON TES 430; a cool FREON TES rinse 432; and vapor displacement drying in warm FREON TES 434.

Application of ultrasonic power is particularly
10 useful in scouring the newly-applied fine cross-texturing grooves on the disk surface. Stages 420, 424 and 426 combine ultrasonic action in liquids with alkali and aqueous cleaning agents for thorough cleaning. Stage 430 combines ultrasonic action with a degreasing
15 solvent like DuPont's FREON TES.

Multistage cleaning process 435 is preferably performed by a Speed Fam Model MD08 cleaning machine. The Speed Fam model MD08 with certain modifications, is suitable for performing this final cleaning process, to
20 maintain the high level of substrate cleanliness prior to film deposition. Specifically, modifications to the Speed Fam MD08 machine include passivated stainless steel tanks and recirculation lines, brush materials such as polyvinylalcohol, and a highly efficient tank
25 filtration system. In addition, standard process cassette rollers are replaced with highly wear-resistant plastics like DuPont's DELRIN polymethylene oxide. The process regimen 410, as illustrated by Figure 4, was found to be capable of handling approximately 550-750
30 disks per hour, using two Speed Fam model MDS1 polishing machines and one Speed Fam model MD08 cleaning machine. Higher processing rates would result with additional process hardware, but may be limited because of the

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release of FREON TES, a chlorinated fluorocarbon, to the environment.

D. Pallet Design

5 A unique rack or "pallet" for carrying a number of discrete substrates such as disks utilized in Winchester-type hard disk technology will be discussed with reference to Figures 8-11.

10 Generally, a plurality of magnetic disk sizes are manufactured for Winchester-type hard disk drives; two of the most common include 65 mm and 95 mm diameter disks. It will be understood that the general principles of pallet 800, described herein with reference to a pallet for carrying 95 mm disks, are
15 applicable for pallets equally capable of handling disk substrates of other sizes.

 Pallet 800, shown in Figure 8, shows 56 substrate carrying regions 1000 for carrying 95 mm diameter disk substrates 510. A pallet designed to carry 65 mm
20 diameter disk substrates has 99 substrate-carrying regions 1000. Pallet 800 may be manufactured from 6061-T6 aluminum, available from the Aluminum Corporation of America (Alcoa), Pittsburgh, Pennsylvania or other suitable material. Pallet 800 has a height H'' of
25 approximately 34.56 inches, a length L of approximately 31 inches, and a depth DD of approximately 0.25 inch. These dimensions reflect the maximum size pallets or single sheet substrates which may be utilized if sputtering apparatus 10 is made to have dimensions as
30 discussed herein.

 In utilizing pallets having the above-mentioned dimensions, several problems arise. Achieving a uniform temperature profile across the surface of the pallet is difficult, especially where thermal expansion of the

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pallet material occurs at a different rate than that of disk substrates carried therein because of the pallet's greater thickness. Specifically, thermal expansion of the pallet material causes inherent warping of the pallet. Further, thermal expansion reduces the clearance within each substrate-carrying region 1000 around each disk substrate 510, constricting and warping disk substrates 510 undergoing their own thermal expansion, and ultimately precluding uniform film deposition. Addressing thermal expansion incompatibilities between the pallet and disk substrates is more than an issue of material selection. For a high throughput sputtering system, maximizing the substrate-carrying capacity of pallet 800 is equally desirable.

To minimize warping while maximizing the substrate-carrying capacity of pallet 800, substrate-carrying regions 1000 are arranged in a staggered, hexagonal fashion, providing the densest arrangement of disk substrates 510 within the established dimensions of pallet 800. As such, substrate-carrying regions 1000 are arranged in rows 810-880, wherein each substrate-carrying region 1000 in a particular row (e.g., 810) is offset from another substrate-carrying region 1000 in an adjacent row (e.g., 820) by a distance equalling one-half of the total horizontal width of each substrate-carrying region 1000.

In an effort to minimize thermal losses from disk substrates 510 to pallet 800, slots 890 and cavities 895 are provided. Cavities 895 in the lower portion of pallet 800 reduce the surface area of pallet 800 which is subject to thermal expansion, without reducing the substrate-carrying capacity of pallet 800 as the lower portion of pallet 800 does not carry disks beyond the extent of the sputtering flux. Notches 892 compensate

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for nonuniform thermal expansion across pallet 800 as a result of nonuniform heating across the pallet surface. Specifically, notches 892 allow relatively unrestricted expansion of the edges of pallet 800, thereby avoiding pallet warping.

Reference notches 910 in pallet 800 are provided for use with robotic loading and unloading stations 40 and 45. Specific operation of these stations 40 and 45 is discussed in Section E of the specification.

With reference to Figures 10 and 11, details of disk substrate-carrying regions 1000 are hereinafter discussed. Each substrate-carrying region 1000 has a roughly circular orifice with an outer circumferential edge 1010 defined by a beveled edge 1015. Beveled edge 1015 reduces any shielding effect pallet 800 may have on disk substrate 510 mounted in substrate-carrying region 1000 during sputtering. Notch mounting groove 1020 in the lower half of region 1000 allows disk substrate 510 to be seated therein. Lip 1030, at the upper portion of substrate-carrying region 1000, allows manual insertion of disk substrates 510 into substrate-carrying regions 1000. As shown in Figure 10, lip 1030 defines a semi-circular arc 1035 having a radial distance from axis F of 1.9 inches in the 95 mm embodiment of pallet 800, shown in Figures 8-11. Inner edge 1040 is defined by one end of beveled edge 1015 and has a radial distance from axis G of approximately 1.859 inches. Groove 1020 likewise has a semi-circular shape and is positioned a radial distance of 1.883 inches from axis G. Groove 1020 has a depth D' of approximately .012 inches.

In practice, disk substrate 510 is seated in groove 1020 and is securely held in place therein. During processing, pallet 800 is relatively stable and disk substrate 510 is securely maintained in substrate-

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carrying region 1000. The radial distance between axis F and axis G is approximately 0.12 inch, and thus the radial distance between lip region arc 1035 and the base of groove 1020 is 3.903 inches, a distance which is greater than the diameter of a 95 mm disk (3.743 inches). This excess space facilitates disk loading and allows for thermal expansion of disk substrate 510 relative to the pallet 800 during the heating process.

It should be noted that pallet 800 may be passed through sputtering apparatus 10 many times before cleaning, especially of grooves 1020, is required to insure substrate-carrying security within substrate-carrying regions 1000. After approximately 100 production cycles, edge 1040 and groove 1020 must be cleaned due to buildup of deposited layers from constant sputtering in sputtering apparatus 10.

E. Substrate Loading

As discussed briefly with reference to Figure 1, disk substrates 510 may be provided in pallet 800 by means of an automatic loading process which preferably occurs at a point along transport system return path 50. Robotic loading station 40 is arranged to load disk substrates 510 into pallets 800 just prior to entrance of pallets 800 into load lock chamber 12. Robotic unloading station 45 is preferably positioned to remove disk substrates 510 from pallets 800 just after exit of pallets 800 from exit lock chamber 30.

In the automatic loading/unloading process of the present invention, an automatic pallet loading station 40 and an unloading pallet station 45 built by Intelmatic Corporation of Fremont, California are utilized. Each station uses three Adept Model One robots, controlled by Adept Model CC Compact Controllers

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and an Elmo Controller operating under conventional control software, tailored for apparatus 10 by Intelmatic Corporation software for controlling the loading processing and sequencing pallet movement.

5 Three robots 40-1, 40-2, 40-3 load pallets 800 in a top to bottom manner, with first robot 40-1 loading the top third of pallet 800, second robot 40-2 loading the middle third of pallet 800 and a third robot 40-3 loading the bottom third of pallet 800. Likewise, three

10 robots 45-1, 45-2, 45-3 unload substrates from pallet 800 in a reverse order to that of robots 40-1, 40-2, 40-3. Specifically, robot 45-1 unloads the bottom third of pallet 800, robot 45-2 then unloads the middle portion of pallet 800 and finally robot 45-3 unloads the top

15 third of pallet 800. Loading and unloading of pallets 800 in this manner ensures that no particulate matter present on pallet 800 or disk substrates 510 falls from the upper portion of pallet 800 to deposit on disk substrates 510 loaded in lower portions of pallet 800

20 during the loading or unloading process.

The Adept Model One robot and Intelmatic software utilize reference notches 910 in pallet 800 to locate the approximate center of each substrate-carrying region 1000. The Adept robots utilize a single finger-type

25 loading mechanism which engages disk substrates 510 by protruding through the center of each disk substrate 510 and lifts and places disk substrates 510 into grooves 1020 within each substrate-carrying region 1000.

Automatic robots 40-1, 40-2, 40-3 and robots 45-1, 45-2, 45-3 in conjunction with the Intelmatic system,

30 have the capability of loading and unloading, respectively, up to 2,500 disk substrates per hour. Sputtering apparatus 10 has a capability of producing 3,000 95mm thin magnetic film coated disks per hour.

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Automatic loading and unloading stations 40, 45 thus represent constraints on production throughput for the present embodiment of the overall sputtering process discussed herein. As will be recognized by those skilled in the art, additional stations may be provided to increase production loading to match apparatus 10 throughput rates.

Pallet 800 may also be manually loaded and unloaded. In manual loading, lip 1030 is used to align the surface of disk substrate 510 with the planar surface of pallet 800 to more accurately provide disk 510 substrate into groove 1020.

F. Pumping System

Sputtering apparatus 10 incorporates a highly efficient, high capacity vacuum pump system, represented schematically in Figure 12. Preparing sputtering apparatus 10 to carry out the sputtering operation described by the present invention requires that the vacuum pump system achieve two purposes. First, the vacuum pump system must furnish a highly evacuated environment for substantially unobstructed paths between the bombarding species and the target surface, and between dislodged target species and the substrates. Second, the vacuum pump system must minimize contaminant circulation inside sputtering apparatus 10 in order to maintain high film integrity. These goals are achieved simultaneously by virtue of the design of the pumping system of the present invention.

The overall vacuum pump system comprises three mechanical or roughing pumps MP1-MP3, with blowers BL1-BL3, and twelve (12) cryo pumps, C1-C12 including seven 8-inch diameter pumps (C3, C4, C6, C7, C9, C10, and C12), four 10-inch diameter cryo pumps (C2, C5, C8, and

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C11) for process isolation, and one 16-inch diameter cryo pump C1. A cryo pump model such as is available from CTI Cryogenics, a division of Helix Corporation of Santa Clara, California, is suitable for use in the pumping system of the present inventions. Eight compressors CY1-CY8 provide helium gas to cryo pumps C1-C12, with: CY1 supplying C1; CY2 supplying C2; CY3 supplying C3; CY4 supplying C5; CY5 supplying C4, C6 and C7; CY6 supplying C8; CY7 supplying C9, C10 and C12; and CY8 supplying C11.

The overall vacuum system also features a network of valves. Five chamber vent valves CV1-CV5 vent the internal environment of sputtering apparatus 10 to atmosphere. Roughing valves RV1-RV5 isolate mechanical pumps MP1-MP3 and blowers BL1-BL3 from sputtering apparatus 10. Chamber vent valves CV1-CV5 and roughing valves RV1-RV5 allow the apparatus 10 to be divided into five sections allowing each individual section to be vented and pumped down as desired, to facilitate maintenance of sputtering apparatus 10. (See Section K, System Control Software.) High vacuum valves HV1-HV12 isolate cryo pumps C1-C3 from apparatus 10 to allow controlled pump-down sputtering apparatus 10 from atmospheric pressure. Valves MP1IV-MP3IV isolate one or more of mechanical pumps MP1-MP3 from the pumping system conduits, allowing flexibility in the number of mechanical pumps operating at a given time. Cryo pump roughing valves CR1-CR12 control contamination out of cryo pumps C1-C12 during a cryopump regeneration.

In operation, mechanical pumps MP1-MP3 and blowers BL1-BL3 perform a pump-down of sputtering apparatus 10 from atmospheric pressure to a level of about 50 mTorr. During the pump-down, high vacuum valves HV1 through HV12 are closed, roughing valves RV1 through RV5 and

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chamber isolation doors D2 through D11 are open and doors D1 and D12 are closed. Pumps MP1-MP3 and blowers BL1-BL3 evacuate sputtering apparatus 10 to a "crossover" point, which has been selected to be between about 50 microns to 150 microns (50 mTorr to 150 mTorr). When the internal pressure reaches the desired crossover point, the system operator, through the electronic control system, closes roughing valves RV1-RV5 and opens high vacuum valves HV1-HV12. Cryo pumps C1-C12, working in conjunction with compressors CY1-CY8, evacuate the system to about 10^{-5} to 10^{-8} Torr (0.01 microns to 1×10^{-5} microns). Argon gas flow is thereafter provided through gas manifolds 2323 into chambers 14-29 to a sputtering pressure about 9-12 mTorr (9-12 microns).

When a pallet 800 loaded with disk substrates 510 is ready to proceed into sputtering apparatus 10 through load lock chamber 12, chamber 12 is at atmospheric pressure, and chambers 14 through 29 are at about 10 mTorr (10 microns). Pallet 800 enters from a class 10,000 clean room environment where robotic loading station 40 is positioned. Because the clean room environment is more sterile than that of load lock chamber 12, nitrogen gas is provided through valve LLSWEEP and a vent valve (not shown) in load lock 30 is opened to create a positive outflow from the clean room into load lock chamber 12, prohibiting contaminants from entering the clean room's environment. Ceramic filters are also provided to trap particulate matter generated when nitrogen backfill is provided through LLSWEEP into load lock chamber 12. Sturdy filters, such as Membralox 0.01 micron sintered alumina filters, available from Aluminum Company of America (Alcoa) Separations Technology, Warrendale, Pennsylvania, resist flexing over many pumping cycles even at pressures higher than

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2000 psi and thereby contribute to the maintenance of a contaminant-free environment within the sputtering apparatus.

After pallet 800 enters load lock chamber 12 and
5 door D1 closes, mechanical pump MP2 and blower BL3
evacuate the load lock chamber 12 down to about
100 mTorr (100 microns). When the crossover point is
reached, D2 opens, allowing pallet 800 to proceed into
10 dwell heating chamber 14 where pallet 800 and disk
substrates 510 will be preheated in preparation for film
deposition. During the heating cycle, some outgassing
from pallet 800 and disk substrates 510 occurs,
particularly if pallet 800 has been recycled, i.e., has
15 passed through sputtering apparatus 10 at least once
without undergoing scheduled cleaning. The carbon
remaining on pallet 800 acts as a sponge for water which
may be absorbed from the atmosphere when pallet 800 is
at any point along return path 50 from a previous
sputtering run. Water outgassed (known as 'drag in') in
20 dwell heating chamber 14 is removed from the internal
environment of sputtering apparatus 10 by 16-inch cryo
pump C1, evacuating dwell heating chamber 14 back down
to about 10^{-5} Torr (0.01 microns). At this time, a
pressure differential on the order of 10 microns
25 (10 mTorr) exists between dwell heating chamber 14 and
passby heating chamber 16. Because such a pressure
differential can destabilize downstream sputtering
processes, argon is used to backfill dwell heating
chamber 14 in order to equalize the pressures, as
30 monitored by Pirani gauge PIR2. Once this pressure
differential is equalized, door D3 opens, permitting
pallet 800 and disk substrates 510 to proceed into dwell
chamber 18. A pump, such as model PFC-1000 from
Polycold Systems of San Rafael, California, connected

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into dwell chamber 18, removes any residual water outgassed from pallet 800 and disk substrates 510, following additional heating performed in passby heating chamber 16. Removal of this residual water is crucial to eliminate oxidation of the chromium target and underlayer in chromium sputtering chamber 20. Pallet 800 and disk substrates 510 continue through sputtering apparatus 10 and the sputtering operation proceeds as described in Section L.

After the multilayer film is deposited, pallet 800 and disk substrates 510 approach exit lock chamber 30 from exit buffer chamber 29. A pressure differential exists between chambers 29 and 30, on the order of that described in connection with dwell heating chamber 14 and passby heating chamber 16. Argon is used to backfill exit buffer chamber 29 to equalize pressures across door D11, as monitored by Pirani gauge PIR15. Once equalization is accomplished, door D11 opens, allowing pallet 800 with disk substrates 510 to proceed through exit lock chamber 30 and out of sputtering apparatus 10.

Periodically, cryo pumps C1-C12 must be cleaned in order to regenerate the cryogenic capacity of the pumps. More specifically, such cleaning involves clearing the cryo pumps of gases frozen therein. For sputtering apparatus 10, cryo pump regeneration typically takes place during machine down-time scheduled for replacing targets in sputtering chambers 20, 26 and 28.

The cryo pump regeneration process of the present invention is discussed more particularly in Section K of this specification. Generally, cryo pump regeneration is initiated by first closing off all of high vacuum pump valves HV1-HV12, opening roughing sieve valves SVIV1-SV115 and turning on sieve heaters SVNTR1-SVNTR12,

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mechanical pumps MP1-MP3 and blowers BL1-BL3. Simultaneously, warm nitrogen (N_2) is fed from supply N_2 through valves NIF1-NIF12 via heaters NIH1-NIH12 to cryo pumps C1-C12. The nitrogen flow defrosts frozen gases in pumps C1-C12 when C1-C12 reach 290°K, pump MP2 and blower BL2 discharge the contents to the atmosphere external to sputtering apparatus 10. Sieve traps SVIV1-SVIV12 and cryo roughing valves CR1-CR12 insure vapors from hydrocarbon pump oils used in the mechanical pumps do not backflow into and contaminate the internal sputtering environment during the regeneration process. By these means, disk substrates 510 already at various stages within the sputtering apparatus are protected from ambient contaminants accompanying subsequent pallets which enter the sputtering apparatus.

G. Transport Mechanism

With reference to Figures 1, 13, 14, and 24, a system for transporting substrates through sputtering apparatus 10 and along return path 50 utilized in the apparatus and process of the present invention, will be hereinafter described.

The transport system of the present invention utilizes a plurality of individually powered transport platforms 2400. Each transport platform 2400 may be individually controlled with respect to motion and speed by controlling a motor assembly (not shown) associated with each platform. Hence, at any given time, only those motor assemblies associated with platforms which are transporting substrates along their lengths at any given time need be powered. Additionally, the transport speed of each individual platform 2400 is user-controlled, with transfer speeds generally selectable within a specific range, allowing substrate transport

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within sputtering apparatus 10 and return path 50 at varying rates. Each transport platform 2400 is provided with one or more proximity sensors (not shown) which output pallet position signals to the electronic control system of the present invention. This allows the electronic control system and the system operator to identify the location of each and every substrate in sputtering apparatus 10 and along return path 50 at any given time. Three such proximity sensors per transport platform 2400 are provided for each of the 19 platforms used in conjunction with sputtering apparatus 10: 17 platforms in chamber modules 12-30 and two additional platforms at entrance platform 210, at the entrance to load lock chamber 12, and exit platform 220, outside exit lock chamber 30. Twenty (20) transport platforms 2400 are provided along return path 50, each such platform stage along return path 50 having one proximity sensor per platform.

With reference to Figures 13, 14, and 24, each transport platform 2400 includes a motor assembly (not shown) coupled to timing chain assembly 1405, including chains 1410 and 1412, and sprocket wheels 1414-1422, mounted on transport beam 1400. An identical timing chain assembly 1405 is located on the opposite side of each transport platform 2400 (as shown in Figure 14).

Generally, sprocket wheels 1421 and 1422 have a single set of teeth and are mounted to beam 1400 to provide tension adjustment for timing chains 1410 and 1412, respectively. Wheel 1416 has a double set of teeth, one set engaging timing chain 1410 and one set engaging timing chain 1412. Timing chains 1410 and 1412 may be manufactured from polyurethane; however, in load lock chamber 12 and exit lock chamber 30, stainless steel timing chains are required due to reduce excessive

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particulate matter generated and circulated during repetitive pump-down and venting cycles when using polyurethane timing chains. Alternatively, stainless steel chains may be utilized throughout the system.

5 Sprocket wheels 1414 and 1418 may have single or double sets of teeth, as needed. Wheels 1414, 1416 and 1418 are coupled to spindles 1430, passing through beam 1400, which are in turn coupled to rubber roller wheels 1435 in cavity 1440 of beam 1400. Sprocket wheel 1420-10 1 is coupled to a spindle 1424 passing through beam 1400 into cavity 1440 to translate the motion of sprocket wheel 1420-1 to sprocket wheels 1420-2 located on the opposite side of transport platform 2400. Wheels 1420 generally have two sets of teeth, one set engaging 15 timing chain 1412, the other set engaging a chain or gear assembly coupled to the motor assembly associated with the particular transport platform for powering timing chain assemblies 1405. Through bores 1425 are provided in beam 1400 adjacent to the upper portion of 20 each transport beam 1400 to allow sprocket wheels 1420 to be positioned at any of three points along transport platform 2400 as the positioning of the motor assembly relative to transport platform 2400 requires.

It should be noted that the distance between wheels 25 1414 and 1416, and the distance between wheels 1416 and 1418, is equal. Further, when assembled into a complete transport system encompassing, for example, both apparatus 10 and return path 50, the distance between 30 respective end wheels 1414 and 1418 on adjacent platforms is equal to the distance from wheels 1414 and 1418 to wheels 1416. Thus, the inter-roller spacing of rubber wheels 1435 is equal through the entire transport system.

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Substrate carrier 1450 is receivable in interior cavity 1440 of transport beam 1400. Substrate carrier 1450 includes E-beam assembly 1452 and substrate mounting member 1454. E-beam assembly 1452 enters
5 cavity 1440 seated atop rubber wheels 1435 and is transported along the path of each platform 2400 when the individual motor assembly for that platform drives gears 1420 into motion. Guide wheels 1445 are provided to ensure alignment of substrate carrier 1450, and
10 especially E-beam assembly 1452, within cavity 1440.

Each transport platform 2400 is mounted to a wall portion 1402 of sputtering apparatus 10 by a cross beam 1404 and hex nuts 1406. Dual insulating members 1460 isolate substrate carrier 1450, and individual transport
15 platforms 2400, from thermal and electrical energy which is transferred to pallet 800 during transport through sputtering apparatus 10. Insulating members 1460 may be manufactured from an insulating material such as DuPont's DELRIN thermoplastic elastomer. Insulating
20 members 1460 are preferably bolted to substrate mounting member 1454 and include a T-shaped mounting pin 1470 for securing pallet 800. Apertures 805 are provided on extensions 807 of pallet 800 to allow pins 1470 to pass therethrough and pallet 800 to be mounted on carrier
25 1450.

Maintaining a contaminant-free environment within sputtering apparatus 10 is crucial to quality control in the provision of multi-layer coatings on substrates. Utilization of an overhead drive transport system in the
30 system of the present invention allows a large variety of substrates to be coated within a single apparatus. However, such overhead systems suffer from excessive particulate generation which may fall from the transport system to contaminate disk substrates carried below.

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The transport system of the present invention is provided with unique shielding to prevent particulate contaminants generated by the overhead transport drive system from entering chamber modules 12-30 of sputtering apparatus 10. As shown specifically in Figure 14, contaminant shields 1480 are bolted on the lower portion of transport platform 2400 in the interior of chamber modules 12-30. Shields 1480 are shaped so as to bar particulate contaminants generated by each transport platform 2400 from the interior of chamber modules 12-30. In addition, E-beam assembly 1452 is specifically designed such that ends 1482 of shields 1480 are interposed in grooves 1453 of E-beam assembly 1452, minimizing entry of particulate matter into the interior of chambers 12-30.

The transport system described herein further minimizes particulate generation by eliminating metal-to-metal contact. This particular feature of the transport system provides excellent electrical isolation of the substrate, thus providing the added advantage of allowing the substrate to be biased during, for example, carbon sputtering in chamber 28, thereby improving the quality of the carbon coating deposited.

Each individual transport platform 2400 can move substrate carrier 1450 at a velocity ranging up to 24 ft/min along the entire transport path. Optimally, transport speeds within chambers 12-30 of sputtering apparatus 10 are adjustable up to 24 ft/min. Adjustment of drive speeds and each transfer platform 2400 is controlled by the electronic control system as discussed in Section K of this specification.

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H. Substrate Heating System

Uniform substrate temperature is crucial to producing a superior thin film by sputtering processes. Figures 15 through 21 illustrate a heating assembly configuration which accomplishes this goal in sputtering apparatus 10.

Specifically, sputtering apparatus 10 includes a heating assembly whose elements are distributed between dwell heating chamber 14, passby heating chamber 16 and dwell chambers 18 and 22.

As shown in Figures 15 through 17, dwell heating chamber 14 features eight horizontal banks 1510A, 1510B, 1510C, 1510D, 1620A, 1620B, 1620C, 1620D of tubular quartz radiant heating lamps 1514. Banks 1510A, 1510B, 1620A and 1620B are housed in one shallow gold-plated stainless steel tray 1512 and banks 1510C, 1510D, 1620C and 1620D are housed in a second shallow gold-plated stainless steel tray 1512. Each bank 1510A, 1510B, 1510C, 1510D includes eleven 1.5 kW lamps 1514 connected in parallel, vertically aligned and interdigitated to overlap lamp ends between the banks. Individual lamps are separated horizontally by a distance of 3 inches. Each bank 1620A, 1620B, 1620C and 1620D includes three 1.5 kW lamps 1514 connected in parallel, horizontally aligned and interdigitated to overlap lamp ends within each bank. Tubular quartz radiant heating lamps such as those commercially available from General Electric Corporation Lamp Division of Albany, New York are suitable for this purpose.

Within each tray 1512, banks 1510A, 1510B, 1620A and 1620B, and banks 1510C, 1510D, 1620C and 1620D are arrayed vertically. Trays 1512 measure 37.5 in. long (l) by 2-5/8 in. deep (d) by 32-3/8 in. wide (w), with one tray 1512 mounted on chamber door 114, and the other

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mounted on rear chamber wall 99. Each tray 1512 is protected from overheating by a circulating coolant fluid provided through cooling lines 1516.

As shown in Figures 18 through 20, passby heating chamber 16 includes ten horizontal banks 1818A, 1818B, 1818C, 1818D, 1818E, 1818F, 1920A, 1920B, 1920C, and 1920D of tubular quartz radiant heating lamps 1514. Each bank 1818A, 1818B, 1818C, 1818D, 1818E, and 1818F features six 1.5 kW lamps 1514 of the same type and mounted in the same fashion as those in dwell heating chamber 14. Individual lamps 1514 are separated by a distance of 2 inches. Each bank 1920A and 1920B features a single horizontally aligned 1.5 kW lamp 1514.

Banks 1818A, 1818B, 1818C, 1920A and 1920B, are arrayed vertically in gold-plated stainless steel tray 1812 and banks 1818D, 1818E, 1818F, 1920C and 1920D are arrayed vertically in a second gold-plated stainless steel tray 1812. With the exception of housing five horizontal banks each, instead of four, trays 1812 are identical in measurement and respective mounting to chamber door 116 and rear chamber wall 100 as trays 1512 in dwell heating chamber 14. Likewise, trays 1812 feature cooling lines 1716 to provide protection from overheating.

The output from banks 1510A, 1510B, 1510C, 1510D, 1620A, 1620B, 1620C, 1620D, 1818A, 1818B, 1818C, 1818D, 1818E, 1818F, 1920A and 1920B, may be set and monitored for individual lamp operating voltages and currents via the electronic controlling system, described fully in Section K, to operate at desired power levels and for desired periods of time. In the present embodiment, heater banks 1510A-1510D, 1620A-1620B, 1818A-1818F, and 1920A-1920D are operated in sets, wherein each set comprises banks 1510A/1510B, 1510C/1510D, 1620A/1620C,

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and 1620B/1620D, operated in parallel. Alternatively, bank sets 1620A/1620C, 1620B/1620D, 1510A/1510C, and 1510B/1510D, may be operated in parallel. Similarly, opposing banks 1818A/1818D, 1818B/1818E, 1818C/1818F, and 1920A/1920D are adjustably controlled in parallel. Preferably, independent control of each bank 1510A-1510D, 1620A-1620B, 1818A-1818F, and 1920A-1920B, may be provided by the electronic control system. Such control of banks 1510A, 1510B, 1510C, 1510D, 1620A, 1620B, 1620C, 1620D, 1818A, 1818B, 1818C, 1818D, 1818E, 1818F, 1920A, 1920B, 1920C, and 1920D facilitates adjustment of heating power to meet the preheating requirements of different substrate materials.

As shown in Figure 21, dwell chambers 18 and 22A and 22B each have two gold-plated stainless steel reflecting panels 2120, one each on opposite chamber walls 118, 122A, and 122B and rear chamber walls 101, 102 and 104. Reflecting panels 2120 measure 34-3/8 in. in length by 28 in. in width by 0.09 in. thick.

The heating assembly cooperates with the other elements of sputtering apparatus 10 to contribute to the overall high throughput and high quality sputtered films produced. Specifically, as pallet 800 proceeds through dwell heating chamber 14, banks 1510A, 1510B, 1510C, 1510D, 1620A, 1620B, 1620C and 1620D rapidly commence heating to warm both sides of disk substrates 510 before film deposition. If, for example, the desired substrate temperature is about 200°C, the heating time in dwell heating chamber 14 is approximately 30 seconds. Heating lamp warmup time is negligible since low power (about 143 W) is delivered continuously to the lamps to keep lamp filaments warm.

In the geometrically uniform array of heating lamps created by banks 1510A, 1510B, 1510C and 1510D, more

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heat is radiated towards disk substrates 510 carried in the center of pallet 800 as compared to disk substrates 510 carried in rows 810, 820, 870 and 880. In combination with efficient heat reflection from gold-plated stainless steel trays 1512, there is a need to equalize across pallet 800 the amount of heat radiated to individual disk substrates 510. Banks 1620A and 1620B serve as 'trim heaters' to boost the amount of heat radiated to disk substrates 510 carried in rows 810, 820, 870 and 880 of pallet 800. Although such trim heaters are not required, through equalization of heat distribution across pallet 800, trim heaters 1620A and 1620B allow control of coercivity of the deposited film to within about 60 Oe.

To further insure uniform substrate temperature prior to film deposition, a second heating cycle is performed in passby heating chamber 16. Pallet 800 enters passby heating chamber 16 through door D3. The electronic control system enables high power input to banks 1818, 1920, for example, through internal software timers or by reading the output of optical sensor SEN10 (shown generally in Figure 12) capable of detecting pallet motion through the sputtering apparatus 10. As pallet 800 begins to depart passby heating chamber 16, the electronic control system reduces the power of those lamps 1514 positioned at the leading edge of pallet 800 or turns off power to those lamps entirely in response to timing parameters incorporated in the electronic control system software, or sensor SEN13, in order to avoid relative overheating of the trailing edge of the pallet 800.

Banks 1818A, 1818B, 1818C, 1818D, 1818E, 1818F, 1920A and 1920B are initiated and will deliver heat for a preset, empirically determined time as monitored by a

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software timer in the electronic control system. In addition, a software delay timer is triggered to control the opening of door D3, allowing pallet 800 to proceed into passby heating chamber 16. As a result, when pallet 800 triggers SEN13 in dwell chamber 18, after a certain period, lamps 1514 on the leading edge of pallet 800 are reduced in power or turned off entirely, depending on the transport speed through dwell chamber 18. In addition, a Mikron temperature sensor (not shown) may be positioned at the entrance of passby heating chamber 16, allowing the system operator through the electronic control system to adjust the power output of banks 1818A, 1818B, 1818C, 1818D, 1818E, 1818F, 1920A, 1920B, 1920C and 1920D to compensate for thermal variations between disk substrates 510 and across pallet 800. In this manner, a uniform temperature profile is established across the surface of pallet 800 and between individual disk substrates 510, thereby avoiding higher coercivities for those substrates positioned on the trailing edge of pallet 800.

Radiative heat losses from pallets and substrates proceeding through sputtering apparatus 10 are minimized by virtue of gold-plated stainless steel reflective panels 2120.

The cooperation of these elements in the heating assembly contributes to the high throughput of sputtering apparatus 10 by promoting rapid and uniform heating of substrates before film deposition. The heating assembly also efficiently maintains the desired substrate temperature by minimizing radiative heat losses as disk substrates 510 proceed through sputtering apparatus 10. Moreover, integration with the electronic control system introduces added flexibility with respect

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to selecting and adjusting dwell times and heating rates as required by different substrates and sputtered films.

I. Sputtering Chambers in General

5 As shown in Figures 1 and 2, the present invention includes three in-line sputtering chambers 20, 26, and 28 to deposit a multilayer film, including chromium, CoCrTa and carbon thin films, respectively. Those skilled in the art will recognize that the application of the following principles to design a sputtering apparatus with greater or fewer sputtering chambers or with the capability to deposit more or fewer films is within the contemplation of the present invention. Moreover, all of the sputtering chambers within a particular sputtering apparatus need not be devoted to sputtering films. Indeed, any given sputtering chamber may participate in the overall process solely to the extent of serving as a pressurized inert passageway for substrates.

20 The following description relates to the internal configuration of each sputtering chamber, which is symmetrical about the line of pallet travel through the sputtering apparatus 10. Figures 13, 14 and 23 through 28 illustrate various aspects of the sputtering chambers and will be referred to as necessary.

25 Referring to Figures 13, 14, 22 and 23, sputtering chamber 20 generally represents the internal configuration of sputtering chambers 20, 26 and 28. By way of explanation, only chromium sputtering chamber 20 will be hereafter described. Only one-half of the chamber is described with the understanding that the description applies to both halves.

30 Four planar (rectangular) cathodes 2222, 2223, 2224 and 2225 are mounted through insulative layer 121 to

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door 120. Door 120 is rotatable about hinge 1326 to allow access to the interior of chromium sputtering chamber 20, for example, for maintenance purposes. Interlocked protective cover 2305 interrupts the power supply to chromium sputtering chamber 20 when door 120 is opened.

Cathodes 2222-2225 may be composed of a material such as copper and measure about 36 inches in length by 5-1/2 inches in width by 1.125 inches thick. Cathodes 2222-2225 are provided with cooling lines 2552 to protect against overheating. Cooling lines 2552 supply a cooling fluid such as water along cooling conduits 2554 in cathode surface 2550.

As illustrated in Figures 14, 22 and 23, targets 2226-2229 are mounted one per cathode 2222-2225, with the target being nearest the line of pallet travel through chromium sputtering chamber 20. Within any given sputtering chamber, the composition of all four targets depends upon the film to be deposited, but may be chromium, a magnetic alloy or carbon. Likewise, the thickness of the targets depends upon the type and the thickness of the film to be deposited. In the case of the chromium and magnetic sputtering chambers 20 and 26, the target-to-substrate distance 'a' is about 2-3/4 inches and the target-to-substrate distance 'a' for carbon targets is 2-11/16 inches because the chromium and magnetic targets are thicker than the carbon target.

Referring now to Figures 21 through 24, shields 2230, 2236, 2238 and 2240 are mounted one per cathode 2222-2225. Shields 2230, 2236, 2238 and 2240 may be composed of a material such as copper and are generally rectangular in shape with peripheral flanges 2232 and 2234. Shield extension 2231 extends from shield 2230 into the chamber interior. Shields 2230, 2236, 2238 and

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2240 are cooled by cooling lines 2336. A combined anode and dark space shield 2338 is incorporated into each shield 2230, 2236, 2238 and 2240.

5 The sputtering process occurs with the targets sputtering in a sideways fashion, depositing the desired film on each side of disk substrates 510 as pallet 800 proceeds through each sputtering chamber. As Figures 27A and 27B show, during sputtering, flux (represented by vectors \bar{A} and \bar{B}) leaves the target surface diffusely, 10 depositing on the disk substrates and other surfaces within the sputtering chamber. As discussed previously, in-line sputtering of disk substrates can introduce undesirable magnetic anisotropies into the deposited film. Shields 2230, 2236, 2238 and 2240 intercept the 15 obliquely incident flux (vector \bar{A}) from targets 2226-2229 such that only flux substantially normal to the surface of target 2228 (vector \bar{B}) is deposited on disk substrates 510. Specifically, peripheral flanges 2232 and 2234, extending the length of each shield, project 20 toward the line of pallet travel through any given sputtering chamber. Shield 2230 also features shield extension 2231 which similarly projects toward the line of pallet travel. Peripheral flanges 2232 and 2234 and shield extension 2231 block deposition from high- and 25 low-angle flux (vector \bar{A}) as disk substrates 510 enter and exit each sputtering chamber, while providing an unhindered path for normal flux (vector \bar{B}) to the substrates.

30 Figures 25 and 26 illustrate the configuration of cathode 2222 in more detail. Cooling lines 2552 discharge cooling fluid along surface 2550 in shallow channels 2554 and an O-ring (not shown) disposed in channel 2556 prevents coolant leakage outside of channels 2554. On the reverse side of cathode 2222,

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surface 2658 is adapted to receive screws in holes 2660 for mounting cathodes 2222-2225 onto chamber doors 120-1 and 120-2. Surface 2658 is configured to support and receive a magnet and magnetic pole piece assembly to produce the desired magnetic field. The assembly is created in a network of channels in surface 2658 consisting of center channel 2662, intermediate circumferential channel 2664 and outer circumferential channel 2666. Channels 2664 and 2666 are configured as concentric closed loops or ovals surrounding center channel 2662.

Typically, target utilization in sputtering operations are about 15-20% for nonmagnetic materials and about 30-35% for magnetic materials. Considering the high costs associated with the purchase and replacement of target materials, optimal target utilization is another prime concern in sputtering operations. Magnet and magnetic pole piece assemblies used in the present invention substantially improve target utilization, enhancing both production throughputs and cost-effectiveness.

Figures 27A and 27B illustrate in greater detail the magnet and magnetic pole piece assemblies for nonmagnetic (e.g., chromium and carbon) and magnetic (e.g., CoCrTa) targets, respectively. Each magnet 2768 is 1-inch long by 5/16-inch wide by 3/16-inch thick and magnets 2769 are 1-inch-long by 5/16-inch wide by 3/8-inch thick, with north and south pole directions indicated by arrows pointing up and down, respectively. Ferritic magnets of neodymium, iron and boron (NeFeB or "Neo iron") are preferred in the present invention.

Along with magnets 2768 and 2769, magnetic pole pieces 2770 and 2774 are arrayed in channels 2662, 2664 and 2666. Magnetic pole pieces 2770 may be adapted to

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receive screws therethrough for securing the magnet and pole piece assembly within the channels as necessary. A nonmagnetic material 2772, such as aluminum in block or continuous form, is positioned so as to fill the channels as necessary and preclude shunting of the magnetic flux between adjacent magnetic pole pieces 2770. Iron plate 2274 serves as a backing plate for the magnetic and pole piece assembly.

For a nonmagnetic target layout, center channel 2662 of each cathode contains about 25 magnets 2769 separated by 1/4-inch spaces and 25-inch pole piece strips 2770 above and below magnets 2768. Intermediate circumferential channel 2662 contains about 35 magnets 2768 separated by 1-inch spaces, two 31-inch pole piece strips 2770, two 31-inch pole piece strips 2774 adjacent to aluminum filler 2772 with additional pole pieces 2770 for fitting the cropped corners of intermediate channel 2664. Outer circumferential 2666 contains about 33 magnets 2769 and two 33-inch pole piece strips 2770 with additional pole pieces 2770 for fitting the cropped corners of outer circumferential channel 2666. The overall effect of the magnet and the pole piece assembly for the nonmagnetic target shown in Figure 27A is to produce a magnetic field strength above the target surface of 400 Gauss at the center of the erosion region.

For a magnetic target layout, center channel 2662 contains about 25 magnets 2769 with one overlying 25-inch pole piece 2770. Intermediate circumferential channel 2664 contains about 35 magnets 2768 overlaid with two 31-inch pole pieces 2770 and additional pole pieces 2770 for fitting the cropped corners of intermediate channel 2664. Aluminum filler material 2772, in block or continuous form, occupies remaining

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vacancies in intermediate channel 2664. The overall effect of the magnet and pole piece assembly for a magnetic target shown in Figure 27B is to produce a magnetic field strength of about 400 Gauss at the center of the erosion region.

As noted above, the purpose of the magnetic field is to trap electrons and ionized species in the plasma and enhance the sputtering rate induced by the circulating plasma above the target surface. The magnetic field 2700 generated by the magnet and magnetic pole piece assemblies used in the present invention approximate an ideal magnetic field 2700 where the vertical components of the magnetic fields above the nonmagnetic (Figure 27A) and magnetic (Figure 27B) targets are reduced. As a result, greater target utilization is obtained since the magnetic fields and plasma are focused across a relatively greater portion of the target surface.

Target utilization may be further improved by increasing the magnet loading density within the channel network. For example, by loading intermediate channel 2664 with 24 magnets 2768 separated by 1/2-inch spaces, nonmagnetic target utilization increases to between 50% and 65%. For magnetic targets, an increased utilization of between 35% to 50% may result.

Figure 28 illustrates the film structure which may be produced by the present invention on nickel-phosphorus plated aluminum disk substrate 510. A 800Å to 2000Å (1000Å preferably) chromium underlayer 2800 is deposited first on disk substrate 510. A 500Å to 850Å CoCrTa magnetic layer 2802 may be deposited over the chromium underlayer. As a result of the circumferential texturing of the disk surface as discussed previously in Section C.2, the 'C' axis of the hcp structure of the magnetic cobalt alloy is aligned in the film plane.

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Finally, a 350Å carbon overlayer 2804 may be deposited, incorporating some hydrogen, as discussed in Section J.

J. Carbon Sputtering

5 Sputtering chamber design in sputtering apparatus
10 for carbon films requires additional refinements to
optimize wear and corrosion resistance properties.
These refinements are discussed herein with reference
to Figure 13, as necessary.

10 Experiments have shown that the incorporation of
hydrogen into sputtered carbon films improves wear-
resistance properties. In sputtering apparatus 10,
hydrogen incorporation is achieved by sputtering in an
argon atmosphere containing up to about 15% of a
15 hydrocarbon gas. In particular, carbon films sputtered
in the presence of ethylene/argon or acetylene/argon
showed a 300% improvement in wear resistance as compared
to carbon films sputtered in pure argon atmospheres.
Thus, as compared to chromium and magnetic sputtering
20 chambers 20 and 26, carbon sputtering chamber 28 uses a
gas line for argon/hydrocarbon gas mixture to supply
hydrocarbon gas flow during sputtering.

A second type of chamber refinement in the carbon
sputtering chamber relates to the need for substrate
25 bias. As noted above, during sputtering, primary or
"fast" electrons dislodge from the target and join the
plasma. These fast electrons are constrained to field
lines in the plasma where they may ionize argon atoms or
may be attracted to positively biased regions within the
sputtering chamber. Deposition of dielectric target
30 materials, such as carbon, on surfaces other than the
substrate can reduce the electrical conductivity of
those surfaces and inhibit the electron grounding
thereon. As a result of the reduced electrical

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conductivity, fast electrons either scatter and ionize argon, or are therefor available to impinge on the substrate, whether positively biased or grounded. In the event of the latter, the substrate may be heated
5 sufficiently by electron bombardment to cause graphitization of the growing carbon film.

One means of avoiding graphitization resulting from electron bombardment of the substrate is to apply a negative bias to the substrate to repel any stray
10 electrons. As shown in Figure 13, arcuate phosphorus-bronze fingers 1302 depending from insulating block 1304 and connected to an external voltage source (not shown) provide an electrical contact to pallet 800 by which a negative bias may be applied. More specifically, as
15 pallet 800 proceeds through carbon sputtering chamber 28, phosphorus-bronze fingers 1302 brush against the bottom edge of pallet 800 and establish the desired negative bias. At least one phosphorus-bronze finger 1302 maintains contact with the moving pallet while
20 pallet 800 is in carbon sputtering chamber 28.

A third refinement relates to a reduction of pallet transport speed through carbon sputtering chamber 28. As a target surface is increasingly eroded during sputtering, the once-flat surface eventually develops a
25 depression which mirrors the magnetic field lines. As a result, the magnetic field lines emerging from the target are no longer perpendicular to the electric field lines at the target surface. The significance of the growing erosion region is that during sputtering, target
30 species continue to leave the erosion region in a path perpendicular to the surface, i.e., according to a cosine distribution, even where the eroded target surface is no longer uniformly flat. Therefore, an increasing portion of the flux leaving the target

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surface is intercepted by shields 2230 as otherwise obliquely incident flux. In other words, a correspondingly decreasing portion of the flux is deposited on disk substrates 510 (and pallet 800) as the
5 desired normally incident flux, thereby decreasing the overall film deposition rate. In general, such a decrease in deposition rate may be compensated for directly by increasing the power supplied to the cathodes. For carbon targets, it has been discovered
10 that this method of compensation is impracticable because increased power input to and resultant heat from the cathodes would induce undesirable graphitization.

The carbon target is also altered by redeposition of carbon from the flux into the erosion region.
15 Specifically, since carbon is a dielectric material, such redeposition reduces the electrical conductivity of the target, further decreasing the carbon sputtering rate and may cause arcing. For conductive target materials like metals, redeposition is not similarly
20 problematic.

Accumulations of the redeposited carbon, which appear as large blemishes or warts, may be removed by grinding the carbon surface. However, such a solution to the redeposited carbon problem is time- and labor-
25 intensive, and consequently is not preferred because it detracts from the high throughput capability of the sputtering operation of the present invention. A much more manageable and attractive solution directly minimizes graphitization by holding deposition power to
30 the cathodes constant and reducing the pallet transport speed from the typical rate of 3 feet/minute, via the electronic control system to, for instance, about 2.8 ft/min, to compensate for the lower deposition rate.

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K. Electronic Control System

The electronic control system for sputtering apparatus 10 and the process of the present invention provides one or more system operators with the means to
5 comprehensively and efficiently control production throughput, applied sputtering power, and other sputtering apparatus parameters. The electronic control system is preferably programmable to allow a plurality of different operating parameter settings to be stored
10 for each of the adjustably controlled elements of the sputtering process. Thus, the electronic control system generally performs two major functions: (1) monitoring sputtering apparatus 10 by reading data input from every aspect of sputtering apparatus 10, and providing status
15 data to the system operator(s); and (2) controlling the sputtering process by providing user-controlled and automatically generated control signals to the functional elements of sputtering apparatus 10.

The electronic control system of the present
20 invention will be described with regard to Figs. 12, 29 and 30. Figure 12 is a diagram of the vacuum and chamber pumping system of the present invention, including general representations of the location of the various signals and components controlled, or read by,
25 the digital input/output of programmable logic controller 2902. Figures 32A-B represent a logical flow diagram of the programmable logic software controlling the motor assemblies powering transport platform arranged in chambers 12-30 in apparatus 10 of the
30 present invention.

Referring to Figure 29, the major functional elements of the control system of the present invention are shown. Since both digital and analog input/output must be provided for in one embodiment, two main process

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controllers are used: a programmable process logic controller 2902, preferably an Allen Bradley PLC-5 programmable process logic controller, and an IBM-compatible, Intel-type 80386 or 80486 microprocessor based, computer 2901. It should be understood by those skilled in the art after review of the specification that the particular choice of process controllers is not crucial to the invention, as long as the process controller(s) can sufficiently handle input/output (I/O) in both analog and digital form to meet the comprehensive requirements of the control system described herein.

The Allen Bradley PLC-5 is manufactured by Allen Bradley Company, Milwaukee, Wisconsin, and includes at least one PLC-5 processor module and a number of input/output modules attached thereto. The input/output modules provide an expandable number of inputs and outputs to handle any number of digital I/O signals.

Programmable logic controller 2902 monitors digital input and provides digital output to those elements of the sputtering apparatus which require two-state control signals. These elements are described in detail below. Allen Bradley PLC-5 uses logic control software configured as "ladder" logic table diagram, a copy of which is included in Section M, to control input and output. In general, this software allows programming of the sensory input and output in a Boolean-type fashion along a series of horizontal timing "rungs". The entire "ladder" is scanned, top to bottom, every .030-.040 second, and each addressed element of I/O is examined by the processor. Each rung is programmed with both internal and external I/O, and generates an output command -- either internal or external -- if each element in the horizontal rung is "true". In this

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manner, it will be recognized that horizontally linked elements are ANDed together, while vertically linked elements are ORed. Each rung may be cross-referenced and nested to other individual rungs to achieve the
5 desired logical output. The output of each rung may comprise an "enable," "latch" or "unlatch" signal, depending on the nature of the timing utilized in the particular program.

Computer 2901 primarily controls analog input/output
10 to the various elements of sputtering apparatus 10 via a SIXNET network interface 2903, such as that manufactured by Digitronix SIXNET, Inc., Clifton Park, New York, although some digital input/output functions are handled by the computer 2901. The SIXNET network
15 interface 2403 is coupled to computer 2902 via 307,200 baud SIXNET Model 60-232/N-DL network modem (not shown) coupled to a RS-232 serial port on, for example, a peripheral extension card provided in an expansion slot of computer 2901. Such an extension card may comprise,
20 for example, an IBM Real Time Interface Co-Processor (ARTIC) card manufactured by International Business Machines, Boca Raton, Florida.

In order to handle a sufficient quantity of digital and analog I/O, the network interface 2903 comprising a
25 SIXNET I/O network may include eight SIXNET 60 I/O MUX-FEB multiplex stations, each of which may include two RS-232 serial ports or alternative expansion capability, and sixteen dedicated I/O terminals. The multiplex stations are interlinked by the 307K baud SIXNET network
30 interface. Data I/O of each such station may be configured as the constraints of the physical facility and sputtering apparatus 10 require to couple the necessary I/O signals to the network interface 2903. Network interface 2903 may include SIXNET 60-A/D 16-32

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analog-to-digital converters, 6-D/A 12B-8 digital-to-analog converters, and 6-I032 FET digital/analog input/output modules to handle additional digital and analog I/O as required.

5 Programmable logic controller 2902 and computer 2901 may communicate via a data highway 2911, utilizing an RS-232 serial bus coupled between one RS-232 serial port of the ARTIC peripheral card (discussed above) located in computer 2901, and an Allen Bradley 1171-KF2-B
10 communications interface 2911. Interface 2911 is coupled to programmable logic controller 2902 via serial data highway 2912.

Computer 2901 utilizes a user interface and system control software to monitor, control, generate alarms
15 and store data for apparatus 10. One such software suitable for this purpose is "The Fix", produced by Intellution Corporation, Norwood, Massachusetts. The software allows development of a graphic interface environment for data input/output by creating signal
20 control databases linking the particular interface environment to specific control signals output from, and data sensing signals input to, computer 2901. Thus, input data is transmitted via network interface 2903 from the various components of apparatus 10 to computer
25 2901 to be provided as direct readout to the user I/O environment created using the interface and control software to provide easily readable data to the system operator and/or to create output flags to programmable logic controller 2902.

30 A limited number of output signals are provided by The Fix software to programmable logic controller 2902. These signals comprise combinational results of specific input signals and act as triggers for programmable logic controller 2902. This specific programming code utilized

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in "The Fix" software to generate these signals is included as Section N.

As with the particular process controllers utilized in the present invention, it will be noted by those skilled in the art that the particular software utilized in the process controllers to provide data input/output is not crucial to the substance of the invention; any suitable process control software may be utilized within the scope of the invention to generate any number of suitable user interfaces.

A second, IBM compatible computer 2907 is coupled to programmable logic controller 2902. Computer 2907 may be utilized as a separate programming computer allowing on-line monitoring, debugging, and programming of the ladder logic software in programmable logic controller 2902 utilizing a debugging software, such as that manufactured by ICOM Incorporated, Milwaukee, Wisconsin.

User interfaces are provided for both programmable logic controller 2902 and computer 2901. User interface 2905 coupled to programmable logic controller 2902 may comprise a NEMATRON touch screen, manufactured by NEMATRON, Inc., Ann Arbor, Michigan, which allows data input/output through a series of custom designed, touch sensing, display screens. When utilizing the NEMATRON touch-screen with the Allen Bradley PLC-5, a BASIC module 2906 is provided in the Allen Bradley and coupled to the NEMATRON. The BASIC module is utilized for selecting the display screens on the NEMATRON and for linking particular screen input/output to the data input/output of the Allen-Bradley PLC-5.

Computer 2901 is coupled to user interface 2904, which preferably comprises a standard high resolution graphics display monitor and keyboard. An EGA or VGA

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type high-resolution graphics display, such as the NEC Multisync II, manufactured by NEC Information Systems, Inc., Boxborough, Massachusetts is suitable for use as user interface 2904. Again, it should be understood that any conventional input/output interface may be utilized with the process controllers of the electronic control system while remaining within the scope of the invention.

The electronic control system of the present invention governs three major functions: movement of the substrate through apparatus 10; sputtering process control within apparatus 10; and status indication for apparatus 10. Referring to Figure 29, movement of the pallet 800 and disk substrate 510 through the process is governed by the electronic control system through motor control system 2910, position sensing system 2915, and door control system 2920. Process control and status indication are governed by mechanical pump control system 2925, pump valve and vent control system 2930, cryogenic pump and compressor control system 2935, vacuum valve control system 2940, gas flow control system 2945, gas pressure control system 2950, heater control system 2955, substrate temperature sensing system 2960 sputtering power supply control system 2965, coolant control system 2970, gauge control system 2975 and residual gas analyzers 2980.

With reference to Figure 29, the elements of the electronic control system, and their relationship to programmable logic controller 2902, computer 2901, and network interface 2903 are hereinafter described. It should be understood by those skilled in the art that the elements defined in Figure 29 are arranged in the manner shown for explanation purposes only; various

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modifications of the system are contemplated as being within the scope of the invention.

1. Motor Control System 2910

5 Movement of the substrate through in-line sputtering apparatus 10 is controlled by the substrate transport system, discussed with the reference to Figs. 8-11. As noted therein, each separate transport platform 2400 has a variable speed motor assembly associated therewith and
10 coupled thereto controlling the velocity of the substrate movement at that specific platform in the transport system loop.

With respect to apparatus 10, nineteen (19) individual transport platforms are provided to carry the
15 substrate through the seventeen (17) chambers of sputtering apparatus 10, and load and unload ramps, 210, 212, respectively. Nineteen motors M3-M21 are controlled by three BAM-8 Berkeley Axis Machine (BAM) multi-access servo controllers (not shown). Each BAM-8
20 can simultaneously control up to eight axis of high performance servo motors, and provide multiple, preset, user-defined motor speeds for each axis, allowing digital input signals to activate preprogrammed control sequences for each axis controlled by each particular
25 BAM-8. Each BAM-8 provides eight separate variable voltage output signals, one per axis, to the motor assemblies to control motor speed and, consequently, the velocity of the target substrate at each particular platform in the transport system. Each BAM-8 is
30 preferably coupled by one RS-232 port from one of the eight SIXNET multiplex stations to each BAM-8.

Two sets of nineteen digital outputs from programmable logic controller 2902 provide motor velocity control signals M3F-M21F, M3S-M21S to the BAM-

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8 motor controllers. The two-bit control signal provided by signals M3F-M21F, M3S-M21S allows two individual forward speed settings, start/stop, and, forward/reverse direction to be controlled by programmable logic controller 2902. Nineteen additional digital outputs from programmable logic controller 2902 provide motor interrupt signals M3I-M21I to the BAM motor controllers.

Thirty-eight (38) analog output signals DMOTLO1-DMOTLO21, DMOTHI1-DMOTHI21 are provided for selection of individual motor speed set points of motors M3-M21. The high and low speed setpoints defined by DMOTLO1-DMOTLO21, DMOTHI1-DMOTHI21 define the motor speeds controlled by signals M3F-M21F, M3S-M21S from programmable logic controller 2902; once set, the BAM-8 automatically controls each motor to meet the desired setpoint state. Optimal motor setpoints are listed in Table 1:

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TABLE 1

	<u>Motor #</u>	<u>Setpoints (ft./minute)</u>	
		<u>Fast</u>	<u>Slow</u>
5	M3	12.0	7.5
	M4	12.0	7.5
	M5	12.0	6.0
	M6	6.0	6.0
10	M7	6.0	6.0
	M8	6.0	6.0
	M9	12.0	6.0
	M10	12.0	6.0
15	M11	12.0	6.2
	M12	12.0	6.2
	M13	6.0	6.2
	M14	6.0	6.0
20	M15	6.0	2.7
	M16	6.0	2.7
	M17	12.0	2.7
	M18	12.0	6.0
25	M19	12.0	6.0
	M20	12.0	6.0
	M21	12.0	6.0

Hence, motor control system 2910 provides multiple velocity movement of a substrate through the sputtering apparatus which is useful for controlling a plurality of substrates moving through the sputtering system simultaneously.

2. Substrate Position Detection System 2915

Substrate position detection system 2915 represents the capability of electronic control system to detect and monitor movement of all substrates entering, exiting, or passing through apparatus 10. Fifty-seven pallet position sensors SEN1-SEN57 may be provided in chamber modules 12-30, and entrance and exit platforms 210, 220 to inform programmable logic controller 2902, (and the system operator) of the exact position of each substrate in apparatus 10. Generally, three sensors per pallet platform are provided. Preferably, optical

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position sensors are utilized in chambers 14 and 16 due to their ability to withstand the high temperatures present in those chambers. It should be recognized that it is preferable to provide three sensors per platform for greater accuracy in determining substrate position; in the present embodiment, to improve durability, only two position sensors are utilized in chambers 14 and 16 to reduce sensor failure rates. Each sensor SEN1 - SEN57 provides a digital output signal to programmable logic controller 2902 indicating the presence or absence of a substrate at the sensor's position. Such a comprehensive position detection system provides fault detection in the event a substrate becomes jammed at any point in the sputtering process, permitting the user to compensate for such problems and forestall problems on subsequent substrates in apparatus 10.

Twenty-one additional pallet position sensors (not shown) are provided on the twenty transport platforms utilized in return path 50 (two on the last platform before load station 40). Each such sensor output signal may be provided to programmable logic controller 2902, as shown in Figure 12; alternatively, return path sensor signals may be provided to a separate programmable logic controller.

25

3. Door Control System 2920

Twelve chamber isolation doors D1-D12 are provided to separate certain individual ones of compartment chamber modules 12-30. Each door D1-D12 is operated by a pair of pneumatic cylinders (not shown), each cylinder having a pair of solenoid triggers responsive to DROP and DRCL signals to each cylinder in a direction to open or close the door, respectively. Movement of each of doors D1-D12 is governed and detected by door control

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system 2920. Twenty-four (24) dedicated digital outputs from programmable logic controller 2902 provide pulsed control signals to door open solenoids DROP1-DROP12, and door close solenoids DRCL1-DRCL12.

5 Additionally, door position sensors are provided to detect each door's opened or closed state for the control system software. Door open sensors DROP1S-DROP12S and door closed sensors DRCL1S-DRCL12S provide direct digital output signals to twenty-four (24)
10 digital inputs of programmable logic controller 2902.

 A high pressure air supply (not shown) is used in the sputtering apparatus to provide the requisite air pressure for the pneumatic valves, including door cylinders, high vacuum valves, and other such system
15 components. Primary air sensor APS detects the existence of the high pressure air supply and the absence of a ABS detection signal input to one input of programmable logic controller 2902 initiates a system shutdown override. In addition, eight pressure switches
20 PS1-PS8 are provided to check for the existence of discrete pressure states at various points in the pumping system and apparatus 10. Switches PS1-PS8 redundantly check for a lack of evacuation pressure in pumping conduits in apparatus 10 in the position as
25 shown. Eight digital output signals indicating the detection, or lack thereof, each discrete pressure state are input to programmable logic controller 2902.

4. Mechanical Pump Control System 2925

30 Three mechanical roughing pumps MP1-MP3 and blowers BL1-BL3 provide initial vacuum pumpdown of sputtering apparatus 10, and explosive pumpdown in load lock 12 and exit lock 30 in accordance with the description of the pumping system discussed in section F of this

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specification. Mechanical pumps MP1-MP3 provides high speed pumping up to approximately 20-50 mTorr, while blowers BL1-BL3 provide pumping down to about 1 mTorr before the cryo pumps engage. Mechanical pumps MP1-MP3 and blowers BL1-BL3 thus act in concert to provide rapid pumping of apparatus 10.

On/off controls for mechanical pumps MP1, MP2, and MP3, and blowers BL1, BL2, and BL3, are provided by six digital output signals from programmable logic controller 2902.

5. Mechanical Pump Valve and Vent Control System 2930

Five roughing valves RV1-RV5 isolate mechanical roughing pumps MP1-MP3 and blowers BL1 - BL3 from chambers 12-30 of sputtering apparatus 10. In addition, five chamber vent valves CV1-CV5 allow for venting chambers 12, 18, 22B, 22D, and 30 between the evacuated, sputtering atmosphere and the ambient environment outside apparatus 10.

Mechanical pump valve and vent control 2930 controls roughing valves RV1-RV5, monitored by roughing valve sensors RVS1-RVS10, and chamber vent valves CV1-CV5, monitored by chamber vent sensors CVS3-8. In the absence of sensors associated with any valves, the on/off condition of any valve can be determined by referencing the software output commands (for example, for valves CV1 and CV5).

Thirteen outputs of programmable logic controller 2902 are provided to mechanical pump valve and vent control 2930. A first set of five outputs controls the open/close state of roughing valves RV1-RV5, a second set of five outputs controls the open/close state of chamber vent valves CV1-CV5, and a third set of three

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outputs controls the open/close state of pump vent valves PV1-PV3. In addition, twenty dedicated digital inputs of programmable logic controller 2902 are provided for signals received from roughing valve sensors RVS1-RVS10 and chamber vent valves sensors CVS3-CVS8. Roughing valve sensors RVS1-RVS10 and chamber vent valve sensors CVS3-CVS8 provide state signals to programmable logic controller 2902 to indicate the state of each respective valve CV2-CV4 monitored, thereby allowing the user and the system to more accurately monitor pumpdown and venting of the system. Additional chamber vent valve sensors may be provided on chamber vent valves CV1 and CV5, however because of the high usage of these values, sensor failure occurs rapidly.

6. Compressor and Cryogenic Pump Regeneration Control System 2935

The electronic control system includes a cryogenic pump regeneration and compressor control 2935 which controls the start/stop function of compressors CY1-CY12, nitrogen supply N2, and nitrogen heaters NIH1-NIH12. In addition, cryogenic pump and compressor control 2935 provides on/off control to sieve heaters SVHTR1-SVHTR12 and sieve valves SVIV1-SVIV12, used in flushing contaminants from cryogenic pumps C1-C12 during the cryogenic pump regeneration process discussed above. Nitrogen supply N2 and heaters NIH1 - NIH12 are also used to flush and clean cryogenic pumps C1-C12.

As discussed above in section F of this specification, cryogenic pumps C1 - C12 are provided to create an evacuated environment in chambers 12-30 in accordance with the sputtering process of the present invention. Compressors CY1-CY8 (Figs. 3 and 12) provide helium gas to cryogenic pumps C1 - C12 to enable

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cryogenic pumps C1 - C12 to create the necessary vacuum in sputtering apparatus.

Eight outputs of programmable logic controller 2902 control the start/stop state of compressors CY1-CY8.

5 Eight nitrogen flow sensors NIFS1-NIFS8 detect and insure the presence of nitrogen to nitrogen flow heaters NIH1 - NIH12. Eight programmable logic controller 2902 digital inputs receive flow detection signals from sensors NIFS1-NIFS8. Twelve digital outputs of
10 programmable logic controller 2902 control the start/stop functions for nitrogen heaters NIH1-NIH12. An additional twelve digital outputs of programmable logic controller 2902 provide open/close state control over nitrogen flow valves NIF1-NIF12.

15 Also included in cryo regeneration and compressor control 2935 are sensors, not shown, coupled with cryo pumps C1 - C12 to monitor the temperature of cryo pumps C1 - C12 during the cryo regeneration process and during the sputtering process. Twelve analog network interface
20 2403 inputs receive the analog temperature signals TD1-TD12, over a range of 3°K - 350°K.

Cryo roughing valves CR1-CR12 are provided to control outgassing of cryogenic pumps C1-C12 through sieve heaters SVHTR1-SVHTR12. As noted above, cryo
25 roughing valves CR1-CR12 function in concert with sieve heaters SVHTR1-SVHTR12 in removing contaminants from cryo pumps C1-C12 during the cryo regeneration process. The open/close states of cryo roughing valves CR1-CR12 are controlled by twelve digital outputs of programmable
30 logic controller 2902.

Control of sieve heaters SVHTR1-SVHTR12 and sieve valves SVIV1-SVIV12 is provided by 24 digital outputs of programmable logic controller 2902: twelve (12) digital outputs of programmable logic controller 2902 control

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the start/stop functions of sieve-heaters SVHTR1-SVHTR12; twelve outputs of programmable logic controller 2902 control sieve-isolation valves SVIV1-SVIV12.

5 7. Vacuum Valve Control 2940

Vacuum valve control 2940 provides on/off switching control for, and receives feedback from, high vacuum valves HV1-HV12 coupled between cryogenic pumps C1 - C12, and sputtering apparatus 10. Feedback for high vacuum valves HV1-HV12 is provided by 32 high vacuum sensors HV1S1, HV1S3, HV2S1, HV2S2, HV2S3, ... HV12S1, HV12S2, HV12S3.

High vacuum valves HV2-HV11 are three state (OPEN, CLOSED, and THROTTLE) operation valves. The THROTTLE state is used during operation of the sputtering system to maintain the vacuum level sputtering apparatus, subsequent to initial pumpdown, as the needs of each particular chamber require. High vacuum valve HV1 operates as a two-state (open/closed) valve, and is utilized with baffle 1210. Twenty-four (24) digital outputs (HV1_1, HV1_2, HV2_1, HV2_2, ... , HV12_2) are dedicated by programmable logic controller 2902 to provide twelve, two-bit control signals for high vacuum valves HV1-HV12 and baffles 1210, 1214, to select one of the three states of valve operation discussed above for valves HV2-HV12, or two states for valve HV1, and enable/disable baffles 1210, 1214. Thirty-five (35) digital inputs of programmable logic controller 2902 monitor high vacuum sensors HV1S1 -HV12S3 for respective valves HV1-HV12. One sensor is provided for each operational state of each high vacuum value as applicable.

8. Gas Flow Control 2945

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Gas flow control system 2945 controls the sputtering gas supply for apparatus 10.

Flow control for the primary and secondary gasses, discussed above, may be accomplished through use of eight MKS Instruments, Inc., (Andover, Massachusetts) model 2259B mass flow meters and flow controllers, including MKS model 246 readout displays. Eight isolation valves GF1-GF8 are located between each 2259B mass flow meter and its associated model 246 display. Eight flow control valves FLO1-FLO8 control the flow rate of the primary and secondary gases.

Eight digital outputs of programmable logic controller 2902 are dedicated to control the open/close state of isolation valves GF1-GF8. Computer 2901 receives eight analog input (0-5 volt) flow measurement signals (designated FLO1-FLO8 by "THE FIX") to monitor gas flow via the model 2259B mass flow meters. Flow setpoints of flow controller valves FLO1-FLO8 of the model 2259B mass flow meters are controlled by eight 0-5 volt output signals FLOST1-FLOST8 through network interface 2903 under the control of computer 2901.

9. Gas Pressure Control System 2950

In conjunction with gas flow control system 2945, discussed above, gas pressure control system 2950 monitors and controls pressure in apparatus 10 through a series of four capacitance manometers CM1-CM4, each capacitance manometer CM1-CM4 being separated from apparatus 10 by an associated isolation valve CHV1-CHV4. Each capacitance manometer CM1-CM4 and isolation valve CHV1-CHV4 may comprise, for example, MKS model 390H and 270B capacitance manometers manufactured by MKS Instruments, Inc., supra. MKS model 390H and 270B capacitance manometers include outputs providing analog

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output signals to computer 2901 for monitoring the gas pressure measured thereby, and digital signal inputs to allow for variable control of the metering range of each capacitance manometer or CM1-CM4. Generally, capacitance manometers CM1-CM4 monitor pressure in apparatus 10 subsequent to evacuation of chambers 14-29 by mechanical pumps MP1-MP3. Specifically, gas pressure monitoring during pump-down of apparatus 10 is provided by twenty pirani gauges PIR1 - PIR20; at crossover, the point at which evacuation by mechanical pumps MP1-MP3 blower BL1-BL3 ceases and pumping by cryogenic pumps C1-C12 begins, capacitance manometers CM1-CM4 are used.

Four outputs of programmable logic controller 2902 are dedicated to control open/close states of isolation valves CMV1-CMV4. Four inputs of network interface 2903 receive analog pressure readouts (designated CM1-CM4 by "THE FIX") of capacitance manometers CM1-CM4. Eight discrete outputs of network interface 2903 are dedicated to provide 2-bit digital signals CMR1.1, CMR2.1, CMR1.2, CMR2.2, CMR1.3, CMR2.3, CMR1.4, CMR2.4 to control the pressure metering range of capacitance manometers CM1-CM4.

10. Heater Control System 2955

Substrate heating, including dwell heating in chamber 14 and passby heating in chamber 16, to maintain a uniform temperature gradient over the substrate surface is governed by heater control system 2955. Control of both the "dwell" and "passby" heater banks 1510A, 1510B, 1510C, 1510D, 1620A, 1620B, 1620C, 1620D, 1818A, 1818B, 1818C, 1920A, 1920B, 1920C, 1920D, discussed in Section H of this specification, may be provided by eight Emerson Spectrum III Heater

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Controllers, manufactured by Emerson Industrial Controls, Grand Island, New York. The Emerson Spectrum III controllers allow digital heater temperature setpoint control of the quartz lamp heating elements discussed in section H. Thus, heater setpoints once set will be maintained by each Spectrum III.

In the present embodiment, heater control system 2955 thus utilizes: eight digital outputs of programmable logic controller 2902 providing on/off control signals RH1A-RH3C to the Emerson Spectrum III controllers; eight digital outputs of programmable logic controller 2902 controlling high/low output enable RH1A-RH3C for the Emerson Spectrum III controllers; eight inputs of programmable logic controller 2902 receiving heater fault signals H1A0FLT-H3C0FLT; eight analog outputs from network interface 2903 controlling the voltage setpoints of heater bank sets 1510A/1510B, 1510C/1510D, 1620A/1620B, 1620C/1620D, 1818A/1818D, 1818B/1818E, 1818C/1818F, 1920A/1920B, and 1920C/1920D, and eight analog inputs to network interface 2903 monitoring each heater bank set's current setpoint output HSP1-HSP8.

A preferable embodiment of heater control system 2955 would provide individual control of each of heater banks 1510A-1510D, 1620A-1620B, 1818A-1818D, and 1920A-1920D. Such an embodiment would include additional hardware lines to control each of the heater banks coupled to the electronic control system. In an embodiment using Emerson Spectrum 3 controllers, sixteen such controllers would be utilized and sixteen digital outputs of programmable logic controller 2902 would be needed to provide on/off control signals, sixteen digital outputs of programmable logic controller 2902 would be required to provide high/low output enable

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signals, sixteen additional outputs of programmable logic controller 2902 would be utilized for heater FALSE signals, sixteen analog outputs from network interface 2903 would be needed to control voltage setpoints of the heater banks, and eight analog input signals to network interface 2903 would be utilized to monitor each heater banks current setpoint output.

11. Substrate Temperature Sensoring System 2960

Six Mikron temperature sensors (not shown) may be provided at various locations throughout the sputtering apparatus in a movable configuration to measure the temperature gradient over the surface of the substrate as it proceeds through various sections of the sputtering apparatus. The Mikron sensors provide 0-5 volt analog output signals TEMP1-TEMP6 through network interface 2903 for output to user interface 2904, thereby allowing the system operator to monitor at every cycle and react each heater bank 1818A-1818C output to maintain a uniform temperature gradient across the surface of the substrate as it proceeds through the apparatus. In general, sensors may be provided in chamber 16 or 18.

12. Power Supply Control System 2965

Power supply control system 2965 controls twenty-four (24) designated forty-eight (48) actual, in master-slave configuration), power supplies PS1A, PS1B, ... PS12A, PS12B which provide high power output to the sputtering magnetrons utilized in Chambers 20, 26 and 28 of sputtering apparatus 10. Power supplies PS1A-PS12B may be Model MDX-20X 20KW DC Plasma Power Supplies, Manufactured by Advanced Energy Industries Corporation,

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Fort Collins, Colorado, capable of providing constant current, power, or voltage, and remote control thereof.

Control signals for power supply control 2965 are entirely controlled by computer 2901 through network interface 2903. One hundred sixty-eight inputs of network interface 2903 are utilized as follows:

	<u># of INPUTS</u>	<u>Signal Designation</u>	<u>Function</u>
10	24	PSLS1A-PSLS12A PSLS1B-PSLS12B	read power supply set point level
15	24	PSVO1A-PSVO12A PSVO1B-PSVO12B	read power supply voltage output
20	24	PSC01A-12A PSC01B-12B	read power supply current output
25	24	PSO1A-12A PSO1B-12B	read power supply power output
30	24	PSTL1A-12A PSTL1B-12B	read sputtering target life calculation in power supply
35	24	PSARC1A-12A PSARC1B-12B	read power supply arc detect sense from power supply
40	24	PSSR1A-PSSR12A PSSR1B-PSSR12B	read power supply set point signal reached

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One hundred six analog and digital outputs of network interface 2903 are provided to the power supplies as follows:

5	<u># of INPUTS</u>	<u>Signal Designation</u>	<u>Function</u>
	24	PSSP1A-12A PSSP1B-12B	(analog) power supply level set signals
10	24	PSM1.1-1.12 PSM2.1-2.12	(digital) mode control signals (12 x 2)
15	24	PSON1A-12A PSON1B-12B	(digital) on/off signals (12 x 2)
20	3	PSIV1-3	(digital) indicating vacuum chamber interlocks intact
25	3	PSIW1-3	(digital) indicating water interlocks intact
30	3	PSIX1-3	(digital) indicating heater cover interlocks intact
35	1	PSRES	(digital) emergency stop restore
40			

The aforesaid input signals to network interface 2903, including level set point signals, voltage output signals, current output signals, power output signals, target life signals, arc out signals, and set point reached signals, yield precise data feedback for provision to both the user and the control system

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software to monitor power supply performance. Interlock control signals PSTV1-PSTV3, PSTW1-PSTW3, PSTX1-PSTX3 are coupled to sensors (not shown) on interlock protective covers 2305 of sputtering apparatus 10 to cut out power supply output if the signals are tripped by an open interlock protective cover 2305 thereby preventing operator injury.

13. Coolant Control 2970

Circulating coolant fluid, such as water, is provided to various components of the sputtering apparatus to maintain temperatures within acceptable operating levels during production thereby forestalling rapid depletion of these system components. Specifically, coolant is provided to heaters 1512, shields 2230, compressors CY1-CY8, and sputtering cathodes 2222.

Coolant control system 2970 monitors the temperature level of the circulating coolant flow in the coolant system and controls the open/close states of coolant flow control valves. While the particular layout of the coolant flow system is not shown, it will be understood by those skilled in the art that any suitable number of coolant control schemes may be utilized within the scope of the present invention. The location of coolant flow sensors CHR1A/CHR1B - CHR4A/CHR4B; MAG5A/MAG5B - MAG8A/MAG8B; CAR9A/CAR9B - CAR12A/CAR12B, is shown in general form in Fig. 12.

Coolant flow control 2970 includes 24 magnetron cathode coolant flow sensors CHR1A/CHR1B - CHR4A/CHR4B; MAG5A/MAG5B - MAG8A/MAG8B; CAR9A/CAR9B - CAR12A/CAR12B, six sputtering shield coolant flow sensors CHRS1-CHRS2; MAG1-MAG2, and CARS1-CARS2, and six heat shield coolant flow sensors HSFS1-HSFS6. Each of these sensors

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provides a digital output signal to one input of programmable logic controller 2902. Six water supply flow control valves CHSUV1-CHSUV2, MAGSUV5-MAGSUV6, and CARSUV9-CARSUV10, two supply valves per sputtering chamber, and six water return path valves CHRTV3 CHRTV4, MGRTV7-MGRTV8, CARTV11-CARTV12, two return path valves per sputtering chamber, are provided. Twelve outputs from programmable logic controller 2902 control the open/close states of the water supply valves and the water return path valves.

In addition, two main coolant on valves HH201 and HH202 are controlled by programmable logic controller 2902.

14. Pirani and Ion Gauge Control 2975

Gauge control 2975 also monitors the outputs of each pirani gauges PIR1-PIR20 and ion gauges monitoring residual ion contaminants in sputtering apparatus.

Vacuum pressure during the pumpdown process prior to crossover between mechanical pumps MP1-MP3, blowers BL1-BL3 and cryogenic pumps C1-C12, is monitored by twenty (20) pirani gauges PIR1 - PIR20 provided in the pumping conduits linking cryo pumps C1 - C12 with sieve valves SVIV1 - SVIV12, in chambers 12, 14, 20, 26, 28, 29 and 30 of sputtering apparatus 10, and in the conduit linking pump MP2 and blower BL2 with apparatus 10. Twelve pirani gauges PIR3-5, PIR7-9, PIR12-14 and PIR18-20 monitor pressure during outgassing in the region between cryo pumps C1-C12 to cryogenic roughing valves CR1-CR12. Seven pirani gauges PIR1, PIR2, PIR6, PIR11, PIR16, PIR15, and PIR17 to pressure monitor of chambers 12, 14, 20, 26, 28, 29 and 30.

Analog signals in the range of 0-10 volts are output from gauges PIR1-PIR20 to indicate the measured pressure

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reading of each gauge and are provided to the network interface 2903. Twenty digital signals (designated PIR1 - PIR20) provided to programmable logic controller 2902 inputs to indicate the crossover point set for switchover between mechanical pumps MP1-MP3, blowers BL1-BL3, and cryogenic pumps C1-C12.

Four ion gauges IG1-IG4 (not shown) measure the level of background gas (i.e., water contamination) in chambers 14, 20, 26 and 28 of sputtering apparatus 10. Analog output signals ION1-ION4 are provided by gauge control 2975 network interface 2903 for output to user interface 2904 to provide the system operator with data for controlling the pump-down process.

In the preferred embodiment of the present invention, the pirani gauges and ion gauges are coupled through INFICON gauge monitor subsystems, manufactured by Leybold-Heraeus, Hanau, Germany, which provide an independent power source and hardware for use with the pirani gas and ion gauges discussed above.

20

15. Residual Gas Analyzers 2980

Residual gas analyzers RGA1 - RGA4 are utilized with sputtering apparatus 10 to monitor system status. Isolation of the residual gas analyzers RGA1 - RGA4 is controlled by the electronic control system by means of four isolation valves RGAV1 - RGAV4. Four dedicated outputs of programmable logic controller 2902 are provided to residual gas analyzers RGA1-RGA4 to open and close analyzer isolation valves RGAV1-RGAV4.

Sensors RGAS1-RGAS4 are provided to four inputs programmable logic controller 2902 to provide a status indication of residual gas analyzer valves RGAV1-RGAV4 indicating valve's opened or closed state.

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System Control Software

Figure 30 is an overview flow-chart diagram of the system control software of the present invention. It should be noted that the following description is intended to be a general discussion of the capabilities and functions of the system software. Specific software functions and capabilities will be understood by one skilled in the art after a review of the source code in Sections M and N. It should be further noted that the following discussion does not differentiate between those functions controlled by programmable logic controller 2902 and computer 2901. As will be recognized by those skilled in the art, any of the functions described with respect to Figures 30-32 may be performed by a single process controller or multiple process controllers. The preferred embodiment for performing each of the functions outlined in Figure 30 is shown in Figure 29 and detailed in the source code sections.

As shown in Figure 30, the software architecture is designed to allow both manual and automatic control of select system functions. Certain processes are automated while others depend on comprehensive feedback provided to the user (system operator) allowing the system operator monitor and react to such feedback to make adjustments in particular operating parameters (such as heater power level, and sputtering power supply output levels, etc.) to obtain optimal sputtering characteristics.

In the embodiment of the control software shown in Figure 30, the user or system operator manually controls: gas flow valves GF1-GF8, residual gas analyzer isolation valves (RGAV1-RGAV4); passby and dwell heater setpoints (HSP1-HSP8); power supply and

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motor speed setpoints (PSSP1A-PSSP12B, DMOTLO1-DMOTLO21, DMOTHI1-DMOTHI21); the amount of time spent by a substrate in dwell heater chamber 14 (HTR1TMR); the amount of time the passby heater is on while a pallet is passing therethrough (HTR2ON_DLY); and an emergency stop and pause latch commands.

In addition, other elements such as coolant control, venting control, heater control, power supply control and cryo-pump system evacuation are manually initiated. Specifically, coolant control functions 3070 initiate coolant flow to heater shields 2230 and cathodes 2222-2225 in chambers 20, 26, and 28 upon manual power up of the system. Further, manual control is provided for some heater control functions 3075, such as selection of low and high heater setpoints. Manual control of the heater setpoints allows the user to monitor the output of the (Mikron) substrate temperature sensors and make adjustments to individual heater bank setpoints and/or substrate heating duration timers to achieve an optimal thermal effect on individual substrates moving through heater chambers 14 and 16. Additionally, manual control of some chamber vent functions 3015 allows for apparatus 10 to be vented in whole or in sections for machine maintenance.

Feedback block 3012 provides the user with such data as: argon pressure readout, substrate temperature, power supply output setpoints, motor speed setpoints, an ion & pirani gauge readouts. Additional data, such as that described above with respect to Figure 29, is also provided to the system operator.

Referring to Figure 30, apparatus 10 is generally maintained in a standby state 3028 at full vacuum, e.g., 1×10^{-7} Torr. At system standby 3028, apparatus 10 has been pumped down to a high vacuum level by mechanical

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pumps MP1-MP3, blowers BL1-BL3 and cryopumps C1-C12. The system stand-by condition is usually maintained due to the time required to perform total system pumpdown.

As noted briefly above, system maintenance 3082 may be performed when apparatus 10 is on a section by section basis while venting only those sections necessary for maintenance purposes. In such cases, apparatus 10 is divided into five sections. Generally these sections comprise: chambers 12-14; chambers 18-24A; chambers 22B-24B; chambers 22D-24C; and chambers 29-30. Each of the five sections can be individually vented and pumped down under user control as required, depending on what access to apparatus 10 is required. In this regard, the chamber vent control functions 3015 allow the user to individually control of the opened or closed state of chamber vent valves CV1-CV5 depending on which section is to be vented. Automated section pump sequences 3010 are provided to control roughing down of each section 1-5 using pumps MP1-MP3 and blowers BL1-BL3, and high vacuum valves sequence 3030 to control valves HV1-HV12 as required, to reduce individual sections to high vacuum. Section pump sequence 3010 also ensures that doors D1-D12 are in their required opened or closed states with respect to the pumping or venting of the particular stage as required:

<u>DOORS CLOSED</u>		
<u>STAGE</u>	<u>PUMP</u>	<u>VENT</u>
1	D1 - D3	D1 - D4
2	D4 - D6	D3 - D5
3	D5 - D8	D6 - D7
4	D7 - D10	D8 - D9
5	D9 - D12	D10 - D12

In the instance where chambers 12-30 of apparatus 10 have been fully vented and are at ambient atmosphere, an automated pump down sequence is provided to reduce the pressure of chambers 12-30 to approximately

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50 mTorr. The user initiates the pump down system enable sequence 3020 which provides a check and setup for the pump-down process. A pump down timer PDSTMR is initialized which allows the pump down enable process to
5 run for a maximum of 60 seconds before issuing a fault.

The enable process (PDSE) 3022 comprises: closing RV1-RV5; checking RVS1, RVS3, RVS5, RVS7, RVS9 to ensure valves RV1- RV5 are closed; enabling MP1-MP3; opening
10 doors D2 - D11 (within a limit of 3 seconds before outputting a fault); closing doors D1 and D12; and enabling compressors CY1-CY8. A pirani gauge check 3024 is performed to ensure that PIR2, PIR6, PIR11, PIR16, and PIR15 are less than 125 mTorr (or equivalent preset level between 100-250 mTorr) before the system opens
15 baffles 1210 and 1214. At this point, apparatus 10 has reached a roughed down state 3028 wherein each chamber 12-30 is at a pressure of approximately 50 mTorr, and blowers BL1-BL3 and mechanical pumps MP1-MP3 are disabled (3029).

20 To reduce the pressure in apparatus 10 to a level conducive to sputtering, high vacuum valves HV1-HV12 must be fully opened to allow cryogenic pumps C1-C12 to pump apparatus 10. This sequence 3030 is initiated by a manual user input 3030a assuming the system has
25 reached the roughed, crossover point 3028. At stage 3030, pirani gauges PIR2, PIR6, PIR11, PIR16, and PIR15, corresponding to individual pump sections 1-5, are checked before opening each respective high vacuum valve sets HV1-HV2, HV3-HV5, HV6-HV8, HV9-HV11, and HV12,
30 respectively associated therewith. Once high vacuum valves HV1-HV12 are opened, cryogenic pumps C1-C12 will evacuate the internal environment of chambers 12-30 to a pressure of approximately 1×10^{-7} - 2×10^{-7} Torr.

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When apparatus 10 has achieved a pumped down state 3032, the auto run preparation mode 3034 must be initiated by a manual user input 3032a. Auto run preparation sequence 3034 involves: providing argon backfilling by opening GF3, GF5, GF7, and GF8; checking for no doorfaults (DOORFAULT); check/enable mechanical pumps MP1 & MP3, and blowers BL1 and BL3; check and set dwell and passby heaters to low power setpoints; check and/or set doors D1-D3, D10-D12 closed, and doors D4-D9 open; and throttle HV2-HV12.

Once the system is prepared for auto run mode operation, a user input 3035 is required before the auto run mode 3050 is enabled. If the user input is made and the system is prepared, the auto mode is enabled. Auto mode functions 3050 include throttling high vacuum valves HV2-HV12 and enabling the transport stages of return conveyor path 50. In addition, auto mode 3050 includes the automatic run sequence 3200 controlling motor assemblies, door operation, load/exit lock pumping and venting, and high power supply/heat control described in Figure 32. Sputtering power supplies PS1A-PS12B will have been manually preset to low power. It is noteworthy that coolant control sensors CHR1A-CHR4B, MAG5A-MAG5B, and CAR9A-CAR12B must indicate the presence of circulating coolant in cathodes 2222-2225 before power supplies PS1A-PS12B will be enabled.

Upon exiting auto mode 3050, apparatus 10 returns to a standby state wherein the dwell and passby heaters in chambers 14 and 16, respectively, are automatically switched off and auto run mode is disabled.

The software also provides a number of fault flags to the user to allow the user to correct potential problems or to hold processing of other logic rungs until correction of the fault is completed. Such faults

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may include, for example, argon gas flow failure detection (NO ARGON); a failure in communications between computer 2901 and programmable logic controller 2903 (NO FIX COMM); motor assembly faults; internal
5 system pressure failures (NO VACUUM); cryogenic pump failures (CRYO > 20°K); load lock and exit lock venting problems (LLVENT > 60 s, EXLOCK VENT > 60s); open protective covers on sputtering chambers 20, 26, 28, (INTERLOCKS); mechanical pump and blower failures (MP
10 FAIL); power supply arc (ARC DETECT); air supply failsafe (APS); heater alarm/fault; power supply setpoint alarms; door faults (DOORFAULT); valve faults; and coolant flow faults.

An automated process 3100 for regenerating (cleaning
15 and purging) cryo pumps C1-C12 is also provided in the software of the present invention. Cryogenic pump regeneration process 3100 will be discussed with respect to Figure 31. Figure 31 is a flowchart showing the cryogenic pump regeneration process for a single
20 cryogenic pump, C1. The regeneration processes for pumps C2-C12 are identical, using corresponding valves, gauges, and heaters, coupled to respective pumps C2-C12 as applicable, for each pump C2-C12 being regenerated.

In general, the cryogenic pump regeneration
25 comprises raising the temperature of the cryogenic pumps, supplying the pumps with warm nitrogen, and enabling mechanical pump MP2 and blower BL2 to flush the contaminant materials agitated by the nitrogen flow out of the cryo pumps.

30 Cryogenic pump regeneration process 3100 is manually initiated by a user 3110. User initiation of the cryogenic pump regeneration process preferably enables simultaneous regeneration of all twelve cryogenic pumps 3115. The initial regeneration step 3120 entails

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closing HV1 and initiating a sieve trap timer with a total duration of 5400 seconds.

5 The sieve timer initiates enables sieve heater SIVHTR1 for 3600 seconds (3121, 3122). Further, mechanical pump isolation valve MP2IV is checked and sieve valve SVIV1 is opened (3124) for a duration of 5400 seconds (3126); valve SVIV1 is closed at the expiration of 5400 seconds (3125). In addition, the purge sequence 3130 is initiated.

10 Purge sequence 3130 opens nitrogen flow valve NIF1 and enables nitrogen heater NIH1. Sequence 3130 waits until the cryogenic pump has reached a temperature of 290° K before initiating the purge timer with a duration of 7200 seconds. Purging of the cryogenic pump
15 thereafter continues for 7200 seconds. When complete, NIF1 and NIH1 are closed and roughing sequence 3140 begins.

The roughing sequence involved initially checking to ensure that line pressure (PIR10) is TRUE, BL2 is
20 enabled and PIR3 outputs false (pressure less than 250 mTorr). If these condition are met, cryo roughing valve CR1 and sieve valve SVIV1 are opened, and a roughing timer having a duration of 600 seconds is started. If roughing takes place for longer than 600
25 seconds a fault is generated. Otherwise, the system waits for PIR3 to output a TRUE condition before closing CR1.

After CR1 is closed, a ROR timer waits for 30 seconds to ensure PIR3 remains TRUE. If at any time
30 before the expiration of thirty seconds a PIR3 signal is received, the system counts one and returns to restart the roughing sequence. The system will perform ROR test 3150 generally for up to five cycles (and up to 20 cycles for pump C1) before outputting a fault.

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If PIR3 remains TRUE and the ROR timer = 30 seconds, the process goes to cool down -- allowing 7200 seconds for the cryogenic pump to reach a temperature of $\leq 20^{\circ}\text{K}$. If the cryogenic pump does not reach 20°K within 7200 seconds, a fault is generated.

Figures 32A-32D are a logical diagram of one component of the electronic control system software showing input/output and process control of the auto run mode 3200 controlling substrate movement through apparatus 10. In the logical flow diagram of Figures 32A-32D, horizontal lines indicate software logic flow in relation to time, with time increasing in the direction of the arrows shown therein; vertical lines generally represent decision points.

As shown in Figures 32A and 32D, the system control software of the present invention utilizes motor control 2910, position sensors 2915, door control 2920 and pump valve and vent system 2930, to control movement of a substrate through sputtering apparatus 10. The addresses used in Figures 32A-32D correspond to those discussed above with respect to the functional elements of the electronic control system.

As shown in Figures 32A-32D, start point 3200 in entrance lock loop 3210 of the software represents a system status condition wherein sputtering apparatus 10 is prepared for a substrate to enter load lock 12. Start point 3200 may denote the first substrate entering apparatus 10, or may represent a point wherein a prior substrate cleared load lock 12 and passed into heater 14.

At the start point 3200, roughing valves RV1-R5 are closed, doors D4-D9 are open, doors D1-D3, D10-D12 are closed, and chamber vent valves CV1-CV5 are closed. The software also checks for a TRUE output from PIR17, RV5,

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and DROP10S, indicating, respectively, chamber 30 at crossover pressure, the closed state of roughing valve RV5, and whether door D10 is open.

When a substrate is moved into position at entrance platform 210, the system software is prepared to begin entrance sequence 3210. Position sensors SEN1-SEN3 must indicate a TRUE condition, signaling the presence of a pallet, in order for the software system to proceed. If entrance lock loop 3210 is in a state wherein a substrate has passed out of dwell heater chamber 14, point 3215 in the logic flow line, timer VDDR2CL, which runs for 2 seconds to verify that door D2 has closed, must have completed its sequence in order for processing of that substrate to proceed. Generally, when VDDR2CL is initiated, a substrate will be waiting at entrance platform 210. Thus, input conditions indicated at 3212 will be TRUE and timer VDDR2CL will control initiation of the software logic. After the target position is verified, door close sensor DRCL1S is checked to ensure door D1 is closed, and roughing valve sensor RVS2 is checked to ensure roughing valve RV1 is closed. Additionally, pressure switch PS2 must read FALSE ($\overline{PS2}$), sensor SEN1 is redundantly checked for a TRUE output, and position sensors SEN4-SEN6 must read FALSE to ensure the absence of a substrate in load lock 12. When all the above-mentioned conditions are met, signal OPCV1 is directed to open chamber vent valve CV1 to vent load lock 12. In logical terms, the condition -- DRCL1S AND RVS1 AND $\overline{PS2}$ AND $\overline{SEN4}$ AND $\overline{SEN5}$ AND $\overline{SEN6}$ -- must be TRUE to open CV1, as indicated by the input description 3212. Signal OPCV1 causes pressure switch PS2 to output a TRUE state, and pirani gauge PIR1 to output a FALSE state (e.g., pressure above crossover level).

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A timer CV1_DLY runs for 1 second before a signal is sent to close CV2. Timer PAL_GAT_TT is a 155 second duration timer provided to ensure a specified amount of time passes between the entrance of successive pallets into load lock 12. Timer PAL_GAT_TT is initialized when door D1 is closed, as signified by DROP1 or DROP1S, such signals being generally output after door D1 is closed subsequent to entrance of a substrate into load lock 12, as shown by loop 3214. If PAL_GAT_TT is FALSE (PAL_GAT_TT e.g., timer complete), and PS2, SEN3, and SEN5, are TRUE then signal DROP1 is sent to open outer door D1 to receive a substrate into apparatus 10. Signal DROP1 will cause door open sensor DROP1S to output TRUE, indicating door D1 is, in fact, open. Prior to activating motor assemblies M3 and M4, the logical condition -- (SEN3 or SEN4) AND SEN6 AND DRCL2S -- must be TRUE. When this condition is met, motor assemblies M3 and M4 are activated to move the substrate at high motor setpoint speed from entrance platform 210 of the sputtering apparatus into load lock 12. Movement of the substrate will cause sensors SEN4 and SEN6 to output TRUE, and sensors SEN1 and SEN3 to output FALSE. When sensors SEN3 and SEN6 output FALSE and TRUE conditions, respectively, signaling the presence of the substrate in chamber 14, signal DRCL1 is provided to close outer door D1. Signal DRCL1 causes DROP1S to output a FALSE condition indicating door D1 is closed, and enabling timer PAL_GTE_TT, as discussed above.

Subsequently position sensor SEN6, and door close sensors DRCL1S and DRCL2S, when TRUE, enable timer SOFRUF for 1 second, thereby delaying opening of roughing valve RV1. When timer SOFRUF has completed, and the logical condition -- DRCL1S, P1R1, CV1, BL1, AND

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MPIIVOP -- is TRUE, signal OPRV1 is sent to open roughing valve RV1.

High speed, explosive pumping occurs in load lock 12 until such time as the preset requisite chamber pressure is achieved, causing PIR1 to output TRUE. Opening RV1 causes sensor RVS1 to output TRUE, enabling timer DROP2_DLY to run for two seconds to ensure pump MP1 and blower BL2 have sufficient time to pump load lock 12 down. When timer DROP2_DLY is done and PIR1 is TRUE, RVS1 outputs TRUE and PS2, FALSE. At the same time, signal OPTDR2 is sent to open door D2 to allow the substrate to move between load lock 12 and heater chamber 14.

Before motor assembly M4 will engage, sensor SEN6 must be TRUE, and SEN9 FALSE, to indicate the presence and absence of a target in load lock 12 and heater chamber 14, respectively. If all conditions are met, motor assembly M4 is activated at high speed setpoint; somewhat redundantly, the logical condition -- (SEN6 OR SEN7) AND ~~SEN9~~ -- must be TRUE in order for motor assembly M5 to engage at high speed. A substrate is thereby transferred between load lock 12 and heater chamber 14. The engagement of motor assembly M4 and M5 will cause sensors SEN7-SEN9 to output TRUE, and sensor SEN6 to become FALSE. Simultaneously, if the logical condition -- (~~SEN4~~ OR SEN6) AND DR3CLS, SEN9, AND SEN7 -- is TRUE, signal DRCL2 will be sent to close door D2. Signal DRCL will cause sensor DRCL2S to become TRUE, thereby initiating timer VDDR2CL as discussed above.

At point 3215 in the logic diagram, the software and sputtering apparatus 10 are prepared to receive an additional substrate in load lock 12 while proceeding with the sputtering process on the substrate now present in heater chamber 14. Assuming position sensors SEN1

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and SEN3 indicate the presence of a substrate, loop 3210 will return to start position 3200 and may continuously receive additional substrates while processing of other substrates continues at different points in apparatus 10 in accordance with the following discussion.

At this point, it is notable that the aforesaid redundant signal and sensor readings take on additional significance when multiple targets will be moving through the system. These fail safe sensor readings are provided to ensure smooth operation of apparatus 10, and the absence of pallet collisions or errors within the apparatus.

The substrate present in heater chamber 14 continues through apparatus 10 under the control of the system software as follows. Door close sensors DRCL2S and DRCL3S to ensure doors D2 and D3 are closed. Again, sensor SEN9 is checked to ensure the presence of a pallet in heater chamber 14. If all such conditions are true, HTR1TMR engages for 72 seconds; simultaneously, if no water faults are detected (HSFGIF) heaters 1510A-1510D are driven to high power to act on the substrate present in chamber 14. Heating of the substrate in heater chamber 14 occurs for a specified duration as determined by HTR1TMR.

Upon completion of 72 seconds, two heater timers are initiated: HTRDLYTMR and HTR2ONDLY. If HTR1TMR is completed and no water faults are present (HSFGIF), timer HTR2ONDLY, having a duration of 26 seconds, is enabled to control initiation of passby heaters 1818A-1818F and fault generation signal H2F upon its completion. Simultaneously HTRDLYTMR, having a duration of 25 seconds is enabled and measures out the substrate soak time in dwell heater chamber 14. Upon completion, timer HTRDLYTMR initiates the motor control and venting

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sequence 3220 which runs simultaneously with heater control timing sequence 3225, generally illustrated in Figure 32B. After 25 seconds, baffle 1210 is throttled by signal HV1_2 and timer DR3DT, having a duration of 5
5 seconds, is initiated. If DROP3S is TRUE and timer DR3DT is done, signal DROP3 is provided to open door D3 to allow the substrate to pass from heater chamber 14 into first buffer/passby heater chamber 16.

As will be noted by following parallel processes
10 3220 and 3225, heater banks 1818A-1818E will have been initiated by HTR2ONDLY prior to the substrate's entry into chamber 16 and are timed to remain on until a point at which the substrate is exiting chamber 16. DROP3 will cause door open sensor DROP3S to indicate door D3
15 is in an open state. When the logical condition -- SEN9, SEN13, SEN15 AND DROP4S -- is TRUE, motor assembly M5 is enabled at slow setpoint speed. When the logical condition -- DROP4S, SEN12 AND (SEN9 OR SEN10) -- is TRUE, motor assembly M6 is activated at slow
20 setpoint speed to pass the substrate through from heater chamber 14 first to buffer passby heater chamber 16.

As the substrate is passed through chambers 14 and 16, SEN10-SEN13 will output TRUE and SEN7, FALSE. Subsequently, if the condition -- (SEN11 OR SEN12) AND
25 DROP4S AND SEN15 -- is TRUE, motor assembly M6 is enabled, and if -- (SEN12 OR SEN13) AND DROP4S AND SEN15 -- is TRUE, motor assembly M7 is enabled at slow setpoint speed to pass the substrate from passby chamber 16 into dwell chamber 18. It will be noted that
30 movement of the substrate into chamber 18 triggers SEN13, which in turn initiates timer HTR2OFF. HTR2OFF is set with a duration of 13 seconds, a period which, when used with the motor setpoint speeds set out above (Table 1), shuts off passby heaters 1818A-1818E before

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the substrate fully exits chamber 16. This is to avoid overheating the trailing edge of the substrate, as discussed above. It is further noted that heater fault timer H2F runs for duration of 70 seconds before outputting a fault, indicating that the heater banks have been on too long, possibly resulting in burnout of the heating elements.

In like manner, movement of the substrate through sputtering apparatus 10 by motors M7-M19 continues as shown in Figs. 32C and 32D with associated inputs and outputs shown therein having like affect as the I/O discussed above. Each input condition shown must be met in order to activate subsequent motor assemblies along the substrate's path through sputtering apparatus 10. Likewise, each signal causes an output state change for each sensor or value indicated. In like manner, only those motor assemblies M6/M7, M7/M8, M8/M9, M9/M10, M10/M11, etc., necessary for particular platforms to transport the substrate present at that location are activated. Individual motor assembly speeds are set as discussed in Table 1 to vary the velocity of the substrate through particular chambers of sputtering apparatus 10 as the sputtering process requires. As noted with respect to Figures 32A-32D, and Table 1, motor assembly pairs operate at the same speed in order to assure smooth substrate transport.

As shown in Figure 32D, an exit lock loop 3250, similar to entrance lock loop 3210 discussed above, allows sequential passing of substrates through exit lock chamber 30 to ensure the integrity of the evacuated environment in sputtering apparatus 10 is maintained.

Beginning at point 3252, if -- DRCL10S, CV5, SEN54, AND RVS9 -- are TRUE, (indicating door D10 is closed, chamber vent CV5 is closed, substrate at SEN54, and

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roughing valve RV5 is open, respectively), signal DROP11 is sent to open door D11, thereby causing sensor DROP11S to output TRUE. If -- (SEN51 OR SEN52) AND SEN54 -- then, motor assemblies M19 and M20 are enabled at high setpoint speeds, causing SEN52-SEN54 to be TRUE and SEN51 to be FALSE. Sensor SEN54 enables a signal to close RV5, thereby causing RVS9 to output TRUE, and also enables a signal to close door DR11, causing DRCL11S to output TRUE. A delay timer VDDR11CL delays CV5's closing for 1 second to allow venting of exit lock 30. Once the above conditions are met, and sensor SEN54 is TRUE (pallet in exit lock 30) and DRCL12S is TRUE (door D12 closed), chamber vent CV5 is opened. Subsequently, if roughing valve RVS9 is shown as TRUE, sensor SEN57 indicates FALSE, door close sensor DRCL11S and sensor SEN54 indicate TRUE, and pressure switch PS6 indicates TRUE, exit lock 30 will be vented to atmosphere (opening CV5) and a signal DROP12 will be sent to open door 12, thereby resulting in door open sensor DROP12S outputting a TRUE condition. When pressure switch PS6 outputs a TRUE condition, timer CV5_DLY having a duration of 1 second, will be enabled. Timer CV5_DLY will, upon completion, output a signal to close chamber vent valve CV5.

Once door D12 is open, if sensor SEN54 is TRUE, sensor SEN57 output FALSE, and door sensor DRCL11S outputs TRUE, motor assembly M20 will be enabled to proceed at its fast speed setpoint. Simultaneously, if sensor SEN54 or SEN55 output TRUE, and sensor SEN57 outputs FALSE, motor M21 will be enabled to proceed at its fast setpoint. The substrate present in exit lock 30 will thereafter proceed to exit platform 214.

At point 3260 in the software logic flow, the software branches in two directions, enabling the

- 103 -

substrate to proceed to robot unloading station 45, if the logical condition -- SEN56 OR SEN57 -- is TRUE thereby enabling motor assembly M21 to proceed at its fast setpoint, or looping to prepare to receive an additional substrate in exit lock 30. To prepare to receive an additional substrate, chamber vent CV5 must be closed. Subsequently, sensor SEN54 must output FALSE and door close sensor DRCL11S output TRUE in order for a signal to be sent to close door D12. If the logical condition -- MP3IVOP, CV5, BL3, PIR17, SEN54, AND DRCL11S -- is TRUE, a signal will be sent to open roughing valve RV5 to pump down chamber 30 to prepare for receiving an additional pallet therein. Opening roughing valve RV5 will cause roughing valve sensor RVS10 to output TRUE, and pirani gauge PIR17 will output TRUE when chamber 30 is below crossover. Apparatus 10 is then in a state which exists at software logic point 3252 to prepare to receive an additional substrate in exit lock 30.

As should be understood by those skilled in the art, the particular cross-over pumping levels described above with respect to the software of the present invention may be varied as desired to achieve the requisite atmospheric conditions in apparatus 10 for the particular sputtering application desired. In the preferred embodiment of the present invention, the pirani gauge pressure setpoints outputting digital signals to programmable logic controller 2902 are shown in Table 2:

- 104 -

TABLE 2

		<u>Setpoints (in mTorr)</u>	
		<u>Upper</u>	<u>Lower</u>
5	<u>Gauge</u>		
	PIR1	125	100
	PIR2	125	100
	PIR3	80	50
	PIR4	80	50
	PIR5	80	50
10	PIR6	125	100
	PIR7	80	50
	PIR8	80	50
	PIR9	80	50
	PIR10	1000	50
15	PIR11	125	50
	PIR12	80	50
	PIR13	80	50
	PIR14	80	50
	PIR15	150	125
20	PIR16	125	100
	PIR17	125	100
	PIR18	80	50
	PIR19	80	50
	PIR20	80	50

25 It should be further understood by those skilled in
the art that a multitude of control schemes and sensor
I/O arrangements may be utilized within the scope of the
present invention to provide an automated control
sequence over a substrate or substrates moving through
30 a sputtering apparatus in accordance with the present
invention. The above-described automated run mode 3200
provides for a multitude of pallets, optimally seven
pallets, moving through apparatus 10 as discussed in the
present specification. It should be understood that all
35 such modifications are contemplated as being within the
scope of the invention described herein.

L. Process In General

40 Examples 1 and 2 illustrate process parameters for
sputtering apparatus 10 to produce 950 Oe and 1200 Oe,
respectively, hard drive disks.

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Example 1

As illustrated in Figure 2, once engaged by substrate carrier 1450, pallet 800 loaded with disk substrates 510 proceeds through door D1 into load lock chamber 12. After pallet 800 enters load lock chamber 12, door D1 closes. Load lock chamber 12 is pumped down to 50 microns (50 mTorr) in 20 seconds by mechanical roughing pump MP1. Door D2 opens, allowing pallet 800 to proceed at 6 ft/min into dwell heating chamber 14. Dwell heating chamber 14 has already been evacuated by cryo pump C1 to 10^{-5} Torr (0.01 microns). As pallet 800 proceeds through the chamber, it triggers proximity position sensors which in turn initiate heaters. Heating lamp warmup time is negligible since, during sputtering operations, the lamp filaments are kept warm by a low power level. Pallet 800 and disk substrates 510 soak in dwell heating chamber 14 for 30 seconds with the temperature about 220°C. During this soak period, the heating power applied is 3.1 kW per bank. Argon enters through gas manifolds to backfill dwell heating chamber 14 and equalize the internal pressure before door D3 opens, allowing pallet 800 to proceed. This backfill also maintains pressure equilibrium throughout the apparatus, essential to stabilizing sputtering processes. Door D3 opens to passby heating chamber 16, triggering the initiation of passby heaters. Pallet 800 enters passby heating chamber 16 and after clearing sensor SEN10, triggers the closure of door D3. This chamber also has been evacuated by cryo pump C2 to about 10^{-5} Torr (0.01 microns). Passby heating banks 1818A-1818F operate using 7.6 kW per bank. Lamps 1514 on the leading edge of the pallet reduce power as pallet 800 exits into dwell chamber 18 at 6 ft/min. Pallet 800 proceeds through dwell chamber 18 which has already been

- 106 -

evacuated by cryo pump C3 to 10^{-5} Torr. The pallet proceeds at 6 ft/min past heat reflective panels 2120.

Pallet 800 enters chromium sputtering chamber 20 maintained at 9-12 microns (9-12 mTorr) of argon pressure with argon flow at 300 standard cubic centimeters per minute (sccm). Pallet 800 travels at 6 ft/min as it passes sputtering targets 2226-2229. The sputtering power is 7.5 kW per cathode, with a 1,000 Å thick chromium film deposited. Transport speed through dwell chamber 22A, buffer chamber 24A and dwell chamber 22B is 12 ft/min through open doors D5 and D6. These three chambers are pumped by cryo pumps C4, C5, and C6. Pallet 800 enters magnetic sputtering chamber 26 maintained at 9-12 microns (9-12 mTorr) of argon by cryo pumps C6 and C7 with argon flow at approximately 400 sccm. The transport speed through sputtering chamber 26 is 6 ft/min. The sputtering power is 7.5 kW per cathode, depositing a 800 Å thick CoCrTa film. Transport speed through dwell chambers 22C and 22D and buffer chamber 24B is 6 ft/min. Dwell chambers 22C, 22D and buffer chamber 24B are pumped by cryo pumps C7, C8 and C9. Pallet 800 enters carbon sputtering chamber 28 maintained at 9-10 microns (9-12 mTorr) by cryo pumps C9 and C10 with argon and up to 15% hydrocarbon gas like ethylene or acetylene flowing at 100 sccm. The transport speed is 2.8 ft/min as the pallet passes the sputtering targets in carbon sputtering chamber 28. Sputtering power is 7 kW per cathode with a film thickness of 350 Å. Transport speed through dwell chamber 22E, buffer chamber 24C and exit buffer chamber 29 is 6 ft/min with doors D9 and D10 opening and closing sequentially to allow pallet 800 to proceed. Dwell chamber 22E is pumped by cryo pumps C10 and C11, buffer chamber 24C and exit buffer chamber 29 are pumped by

- 107 -

cryo pump C12. Argon is backfilled into exit buffer chamber 29 by cryo pump C12 to equalize the pressure differential existing with respect to exit lock chamber 30. Pallet 800 next proceeds through exit lock chamber 30 which is vented to the atmosphere by chamber vent valve CV5 in 10 seconds. Pallet 800 then proceeds to robotic unloading station 45.

To produce a 1,200 Oe magnetic film, the soak time in dwell heating chamber 14 may be increased to about 50 seconds to allow the substrate temperature to increase to approximately 250°C and/or the pallet transport speed through chromium sputtering chamber 20 may be reduced in order to allow a thicker deposition of a chromium underlayer. Adjustment of soak time and/or substrate temperature parameters depends on the life cycle of the pallet -- a pallet which has proceeded through numerous sputtering runs will have a thicker film deposition which can absorb more water and consequently would have more water to outgas before film deposition.

The many features and advantages of the apparatus and process of the present invention will be apparent to those skilled in the art from the description of the preferred embodiments and the drawings.

Thus, a high throughput process and apparatus which accomplishes the objectives of the invention and provides the above advantages by providing a comprehensive in-line sputtering system utilizing matched component elements to process multiple large single sheet or pallet transported discrete substrates in a continuous, variable speed, sputtering process has been described. Such an apparatus and method can process up to 3,000 95mm disk substrates, and 5,300 65mm disk substrates, per hour. Such high volume production offers both high volume production and, consequently,

- 108 -

cost savings per disk on the order of \$4.00 per disk over prior art sputtering apparatus and processes. As noted throughout this specification, such an apparatus and process is achieved through a novel combination of process and structural elements involved in disk preparation, provision of a sputtering environment, transportation of substrates through the sputtering environment at rapid speeds and in a contaminant free manner, heating the substrates to optimal thermal levels for sputtering, and sputtering the substrates through a series of substantially isolated, non-crosscontaminating sputtering steps.

109

SECTION M

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110

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Number of Program Files

Name	File	Sub-Program Description	Size:	Elms	Bytes
	0	[SYSTEM DATA STORAGE HEADER]		32	64
MAIH_PRGRM	2	THE MAIN PROGRAM		7205	36456
CRYO_REGEN	3	CRYO REGENERATION RUNGS		1942	10475
RETRN_CNVR	4	THE RETURN CONVEYOR		550	2683
FAULTS	5	THE FAULT RUNGS		798	5114
TECH_RUNGS	6	THE TECHNICIAN RUNGS		370	2578

111

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Rung #000

FIRST SCAN AFTER POWER LOSS 1ST_PASS S:1 15	FIRST SCAN AFTER POWER LOSS PWR_ON_DLY 83 (L) 444
--	---

83/444 - | | - File #2 MAIN_PRGRM - 155
 -|/| - File #2 MAIN_PRGRM - 115, 117, 118, 119, 120, 121, 122, 123, 124, 125, 126, 127, 128, 129, 130, 131, 132, 133, 134, 135, 136, 137, 138
 -(L)- File #2 MAIN_PRGRM - 0
 -(U)- File #2 MAIN_PRGRM - 1

Rung #001

POWER ON DELAY DEFEAT PWR_ON_DLY_DFT 83 268	FIRST SCAN AFTER POWER LOSS PWR_ON_DLY 83 (U) 444
---	---

83/444 - | | - File #2 MAIN_PRGRM - 155
 -|/| - File #2 MAIN_PRGRM - 115, 117, 118, 119, 120, 121, 122, 123, 124, 125, 126, 127, 128, 129, 130, 131, 132, 133, 134, 135, 136, 137, 138
 -(L)- File #2 MAIN_PRGRM - 0
 -(U)- File #2 MAIN_PRGRM - 1

Rung #002

BLOCK TRANSFER WRITE BT_WRITE N11:1 15	BLOCK TRANSFER READ BT_READ N10:0 15	BLOCK TRANSFER WRITE ENABLE BTWRITE BTW BLOCK TRANSFER WRITE Mod Type: 1771-DB BASIC module Rack: 4 Group: 7 Module: 0 Control Block: N11:1 Data File: N7:21 LENGTH: 21 Continuous: N
--	--	--

[2] [3] (EN) (DN) (ER)

N11:1/15 - |/| - File #2 MAIN_PRGRM - 2,3
 N7:21/3 - -() - File #2 MAIN_PRGRM - 532
 N7:21/4 - -() - File #2 MAIN_PRGRM - 533
 N7:21/5 - -() - File #2 MAIN_PRGRM - 534
 N7:21/6 - -() - File #2 MAIN_PRGRM - 535
 N7:21/7 - -() - File #2 MAIN_PRGRM - 536
 N7:21/8 - -() - File #2 MAIN_PRGRM - 537
 N7:21/9 - -() - File #2 MAIN_PRGRM - 538
 N7:21/10 - -() - File #2 MAIN_PRGRM - 539
 N7:21/11 - -() - File #2 MAIN_PRGRM - 540
 N7:21/12 - -() - File #2 MAIN_PRGRM - 541
 N7:21/13 - -() - File #2 MAIN_PRGRM - 542
 N7:21/14 - -() - File #2 MAIN_PRGRM - 543
 N7:21/15 - -() - File #2 MAIN_PRGRM - 544

112

Rung #003

BLOCK TRANSFER BLOCK TRANSFER
WRITE READ
BT_WRITE BT_READ

N11:1 N10:0
15 15
[2] [3]

BLOCK TRANSFER
READ ENABLE
BTREAD

BTR	
BLOCK TRANSFER READ	(EN)
Mod Type:	1771-DB
BASIC module	(DN)
Rack:	4
Group:	7 (ER)
Module:	0
Control Block:	N10:0
Data File:	N7:0
LENGTH:	21
Continuous:	N

N10:0/15 - | | - File #2 MAIN_PRGRM - 2
N7:0/3 - | | - File #2 MAIN_PRGRM - 551
N7:0/4 - | | - File #2 MAIN_PRGRM - 552
N7:0/5 - | | - File #2 MAIN_PRGRM - 553
N7:0/6 - | | - File #2 MAIN_PRGRM - 554
N7:0/7 - | | - File #2 MAIN_PRGRM - 555
N7:0/8 - | | - File #2 MAIN_PRGRM - 556
N7:0/9 - | | - File #2 MAIN_PRGRM - 557
N7:0/10 - | | - File #2 MAIN_PRGRM - 558
N7:0/11 - | | - File #2 MAIN_PRGRM - 559
N7:0/12 - | | - File #2 MAIN_PRGRM - 560
N7:0/13 - | | - File #2 MAIN_PRGRM - 561
N7:0/14 - | | - File #2 MAIN_PRGRM - 562
N7:0/15 - | | - File #2 MAIN_PRGRM - 563

Rung #004

OSCILLATOR
OSC

B3
142
[6]

OSCILLATOR
TIMER 1
OSC_THR1

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:184
BASE (SEC):	0.01 (DN)
PRESET:	50
ACCUM:	0

T4:184.DN - | | - File #2 MAIN_PRGRM - 6

Rung #005

OSCILLATOR
OSC

B3
142
[6]

OSCILLATOR
TIMER 2
OSC_THR2

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:185
BASE (SEC):	0.01 (DN)
PRESET:	50
ACCUM:	48

T4:185.DN - | | - File #2 MAIN_PRGRM - 7

Rung #006

OSC_THR1
T4:184

DN
[4]

OSCILLATOR
OSC

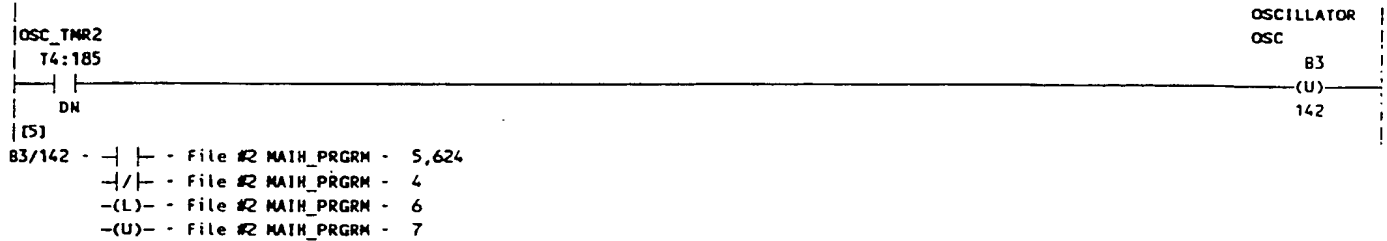
B3
142

B3/142 - | | - File #2 MAIN_PRGRM - 5,624

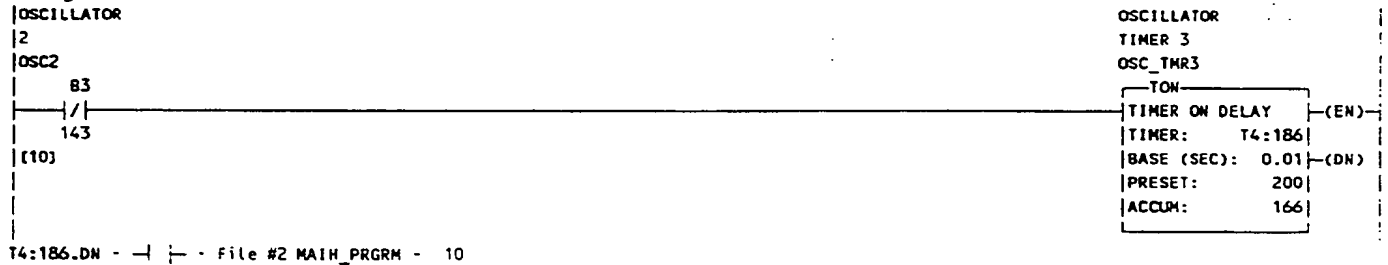
113

-|/|- File #2 MAIN_PRGRM -
 -(L)- File #2 MAIN_PRGRM - 6
 -(U)- File #2 MAIN_PRGRM - 7

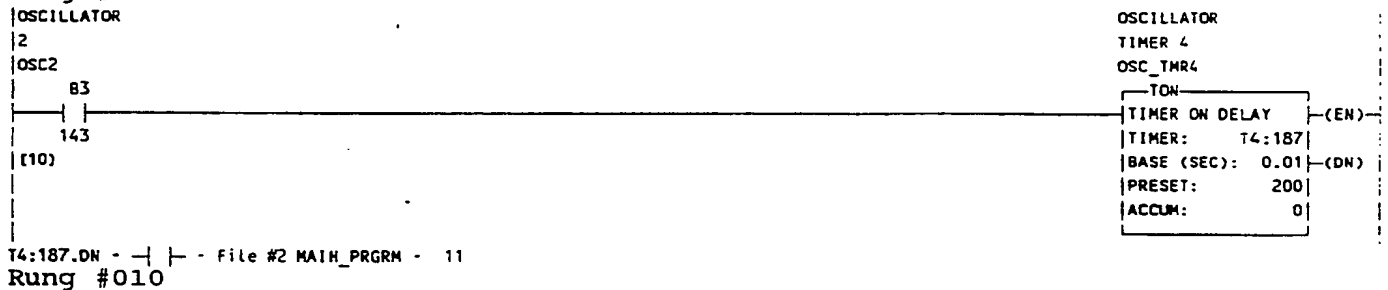
Rung #007



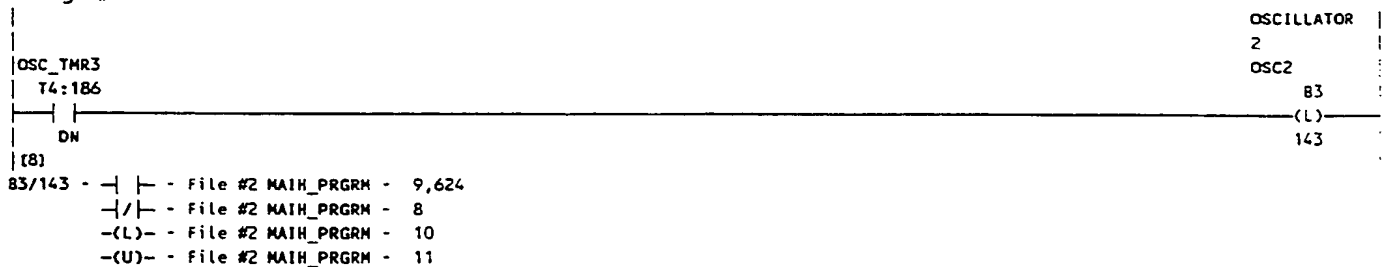
Rung #008



Rung #009



Rung #010



Rung #011



114.

Rung #012

MDPTA

T4:298

DN

[13]

MOTOR DRIVE
PULSER
TIMER B
MDPTB

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:299
BASE (SEC):	0.01 (DN)
PRESET:	5
ACCUM:	6

T4:299.DN - | | - File #2 MAIN_PRGRM - 13,14,184,189,194

Rung #013

MOTOR START

PULSE

MDPTB

T4:299

DN

[12]

MOTOR DRIVE
PULSER
TIMER A
MDPTA

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:298
BASE (SEC):	0.01 (DN)
PRESET:	5
ACCUM:	3

T4:298.DN - | | - File #2 MAIN_PRGRM - 12

Rung #014

MOTOR START

PULSE

MDPTB

T4:299

DN

[12]

MOTOR DRIVE
PULSER
MDP

B3

()

299

B3/299 - | | - File #2 MAIN_PRGRM - 217,230,248,252,257,262,280,284,289,294,305,309,314,319,330,354

-() - File #2 MAIN_PRGRM - 14

Rung #015

AUTO	PALLET	PALLET
MODE	DETECTED	DETECTED
ENABLE	LEFT SIDE	RIGHT SIDE
AUTO	ENTRANCE	ENTRANCE
	SEN1	SEN3

N7:37

11

[155]

MOTOR 3

SLOW

H3S

O:013

02

[187]

0

[13]

Rung #016

SUSPEND

OPERATION

ENABLE

SUSOPE

N7:18

0

[3]

ENTER
PRODUCTION
SYSTEM
LLIN

O:007

()

15

SUSPEND
OPERATION
LATCH
SUSOPL

B3

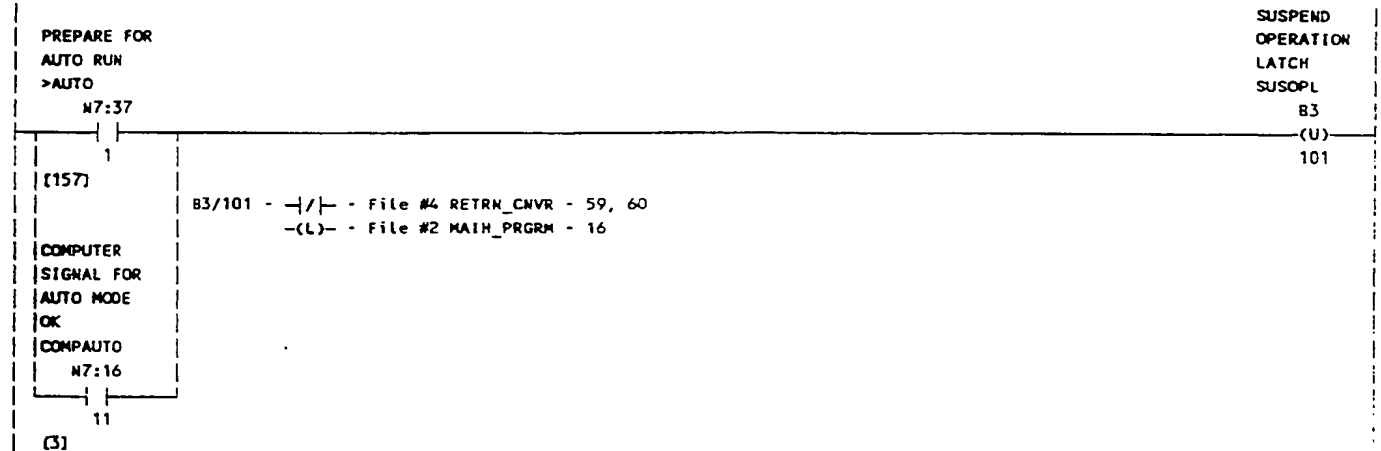
(L)

101

115

83/101 - \neg | - File #4 RETRN_CNVR - ,60
 -(L)- - File #2 MAIN_PRGRM - 16
 -(U)- - File #2 MAIN_PRGRM - 17

Rung #017



SUSPEND
 OPERATION
 LATCH
 SUSOPL
 B3
 (U)
 101

PALLET
 WAITING AT
 MINT EXIT
 PWAME
 0:057
 ()
 14

HIVAC CLOSE
 STAGGER
 HVCL_STAG
 B3
 (L)
 280

HIVAC STAGGER
 TIMER
 HI_STAG
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:197
 BASE (SEC): 1.0 (DN)
 PRESET: 35
 ACCUM: 0

116

Rung #021

ABORT CRYO
REGENERATION
BT_CR

N7:17

9

[3]

HI_STAG
T4:197

DN

[20]

ABORT CRYO
REGEN ENABLE
ABORTCRGM

B3

297

[3:26]

Rung #022

SYSTEM IS
PUMPED
DOWN
SYS_PD

B3

389

[140]

B3/303 - | | - File #2 MAIN_PRGRM - 24, 25, 26, 27, 28, 29, 30, 31, 32,
33, 46, 47, 48, 49, 68, 73, 78, 104, 140, 183, 200,
216, 324, 326, 327, 353, 415
-|/| - File #2 MAIN_PRGRM - 369, 405, 411, 418, 425, 430
-(L)- - File #2 MAIN_PRGRM - 23

N7:36/8 - -(L)- - File #2 MAIN_PRGRM - 23

_f:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

T4:285.TT - | | - File #2 MAIN_PRGRM - 84, 91, 98

ABORT PUMPDOWN

BT_PD

N7:17

8

[3]

PIRINI
GUAGE NO
FAULT
PGNF

B3

465

[5:205]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[157]

HIVAC CLOSE
STAGGER
HVCL_STAG

B3

(U)

280

PUMPDOWN
SYSTEM
ENABLE
PDSE

B3

(U)

303

MANUAL
SYSTEM
PUMPDOWN
ENABLE
MSPE

N7:36

(U)

8

PUMPDOWN
SEQUENCE
DISABLE
PULSE
PDSOPLSE

TON

TIMER ON DELAY

(EN)

TIMER: T4:285

BASE (SEC): 1.0

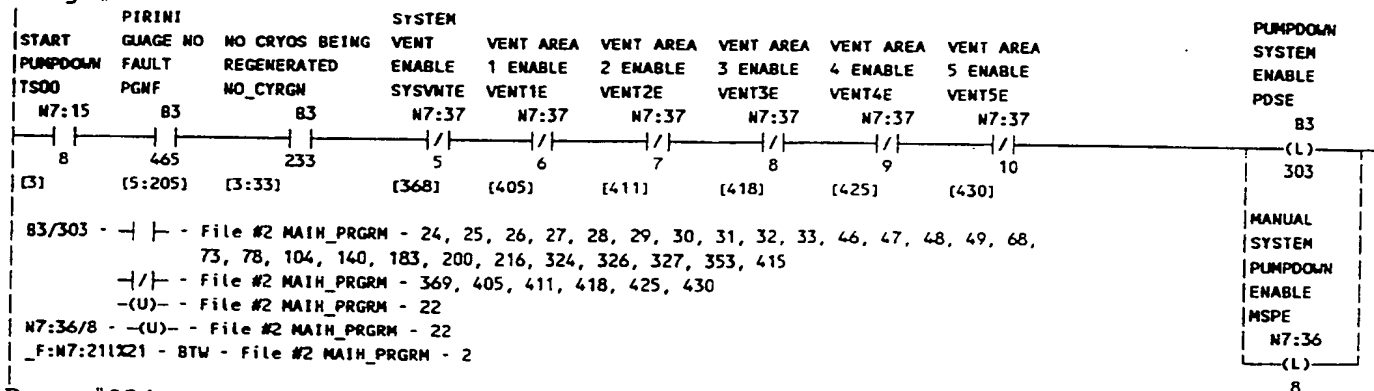
(DN)

PRESET: 5

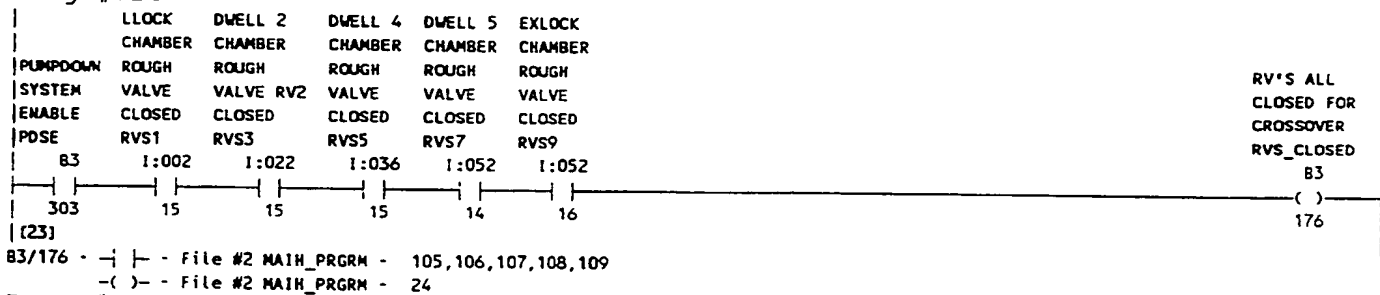
ACQUM: 0

117

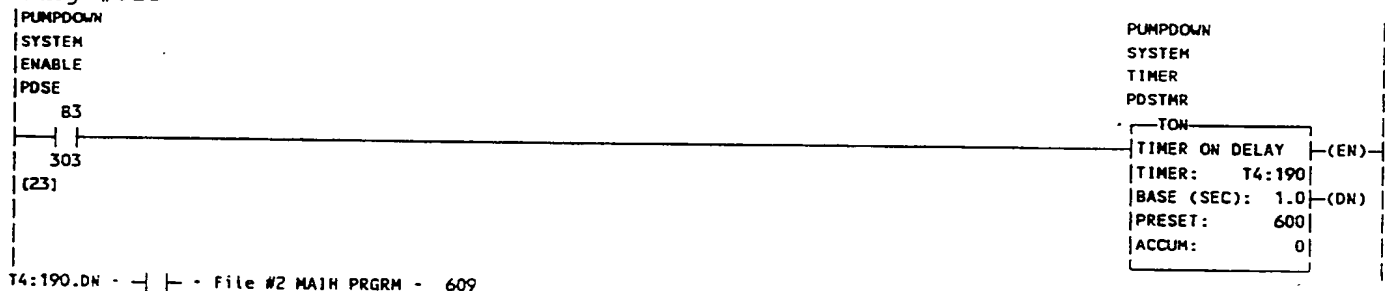
Rung #023



Rung #024

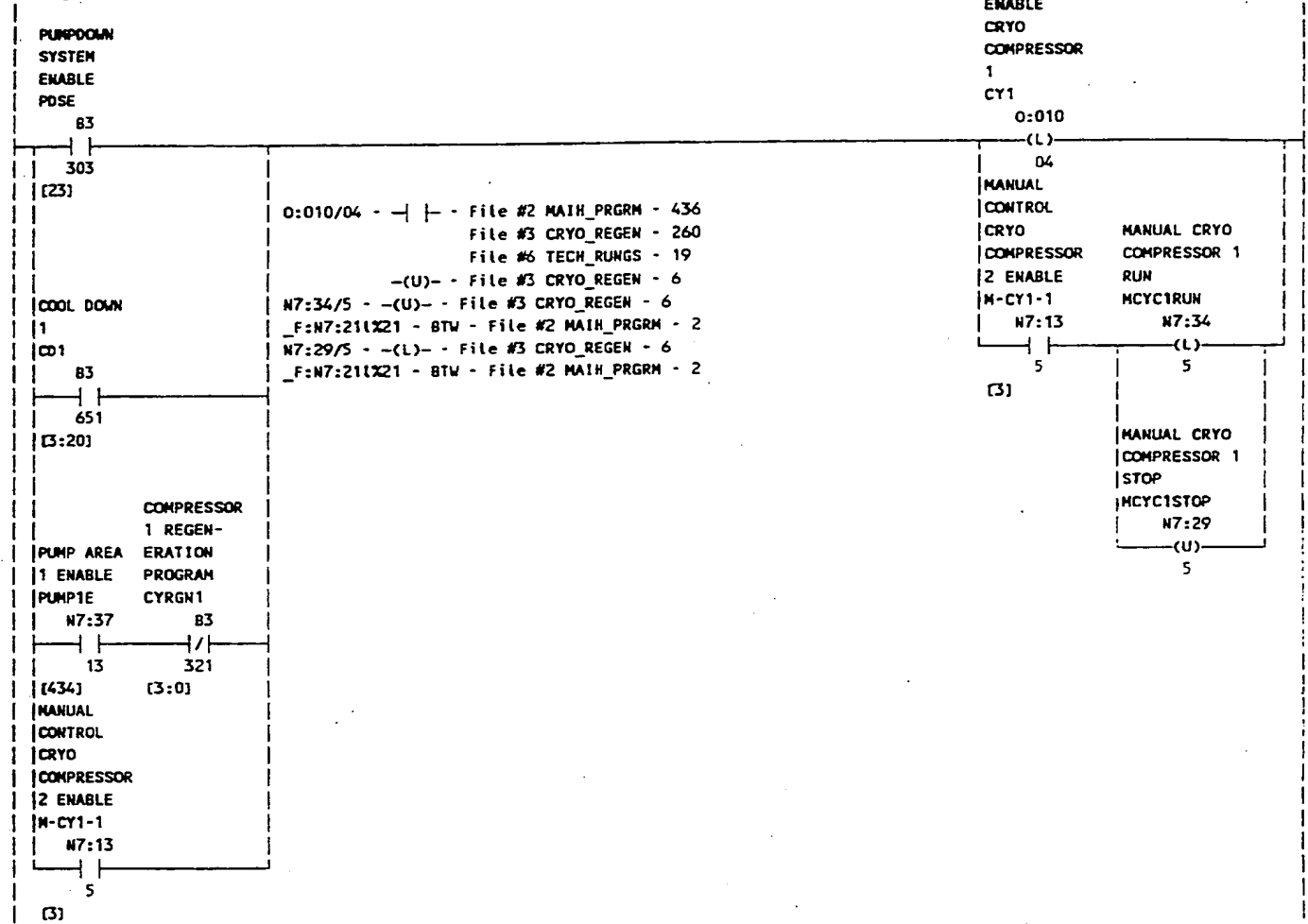


Rung #025



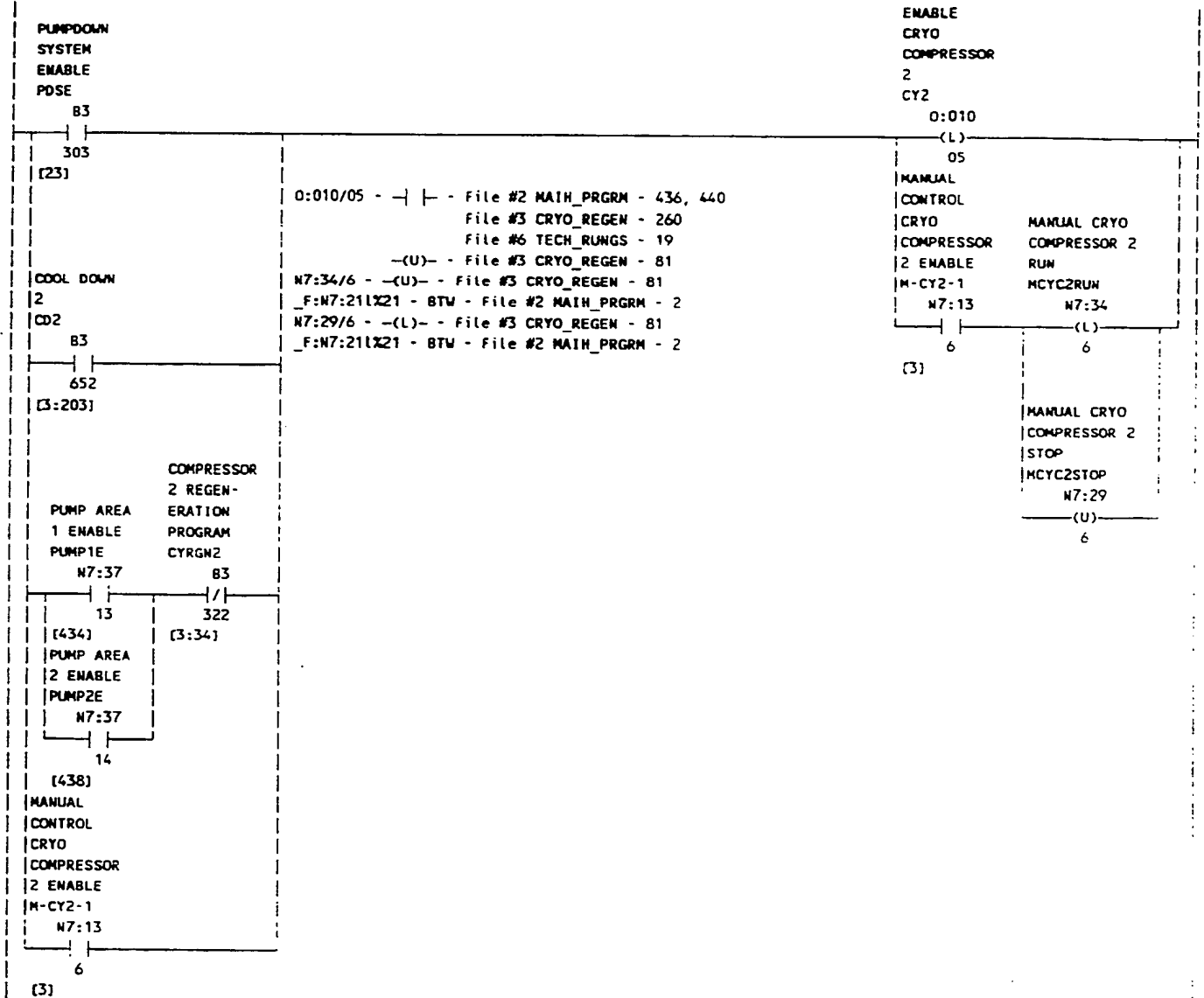
118

Rung #026



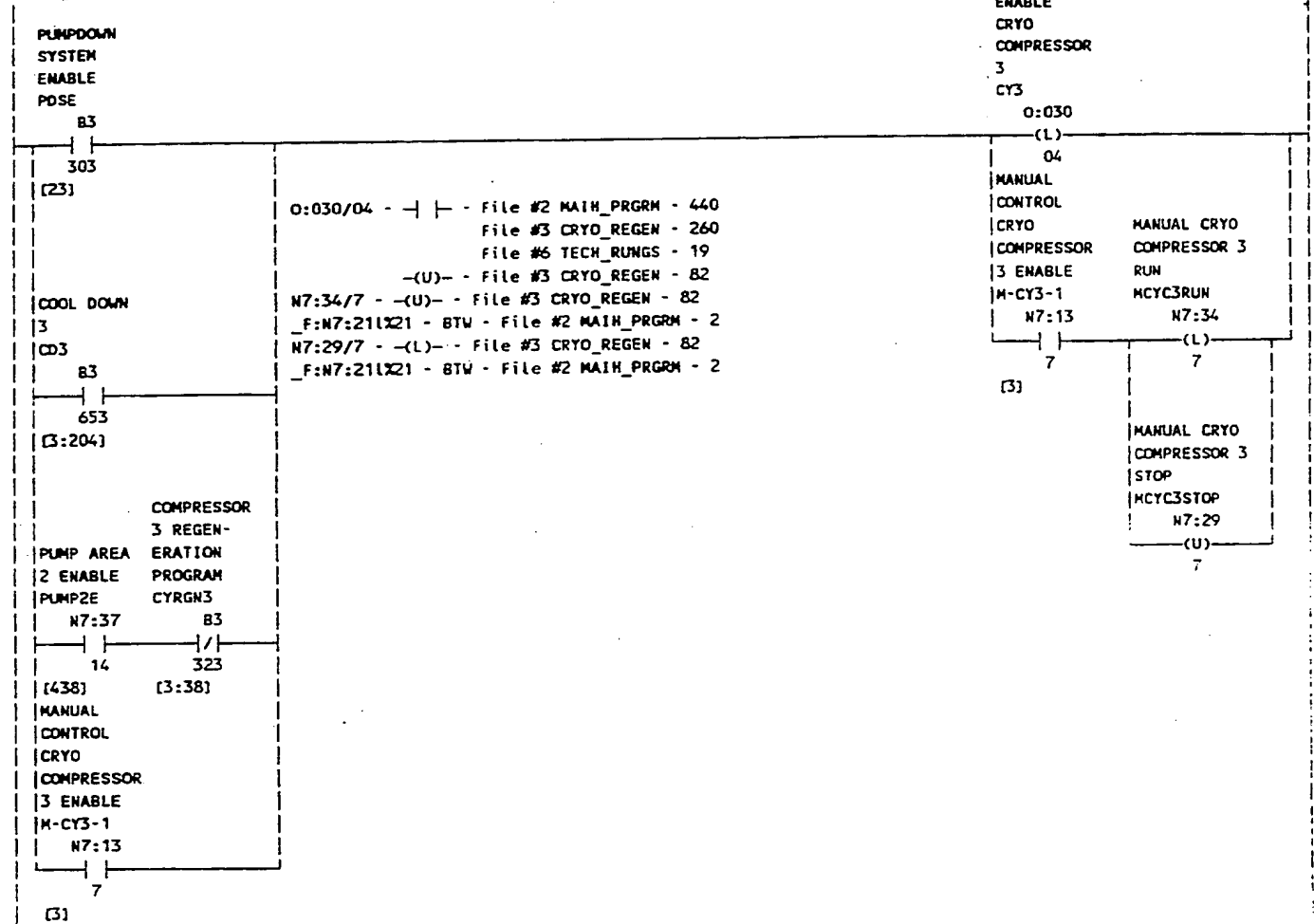
119

Rung #027



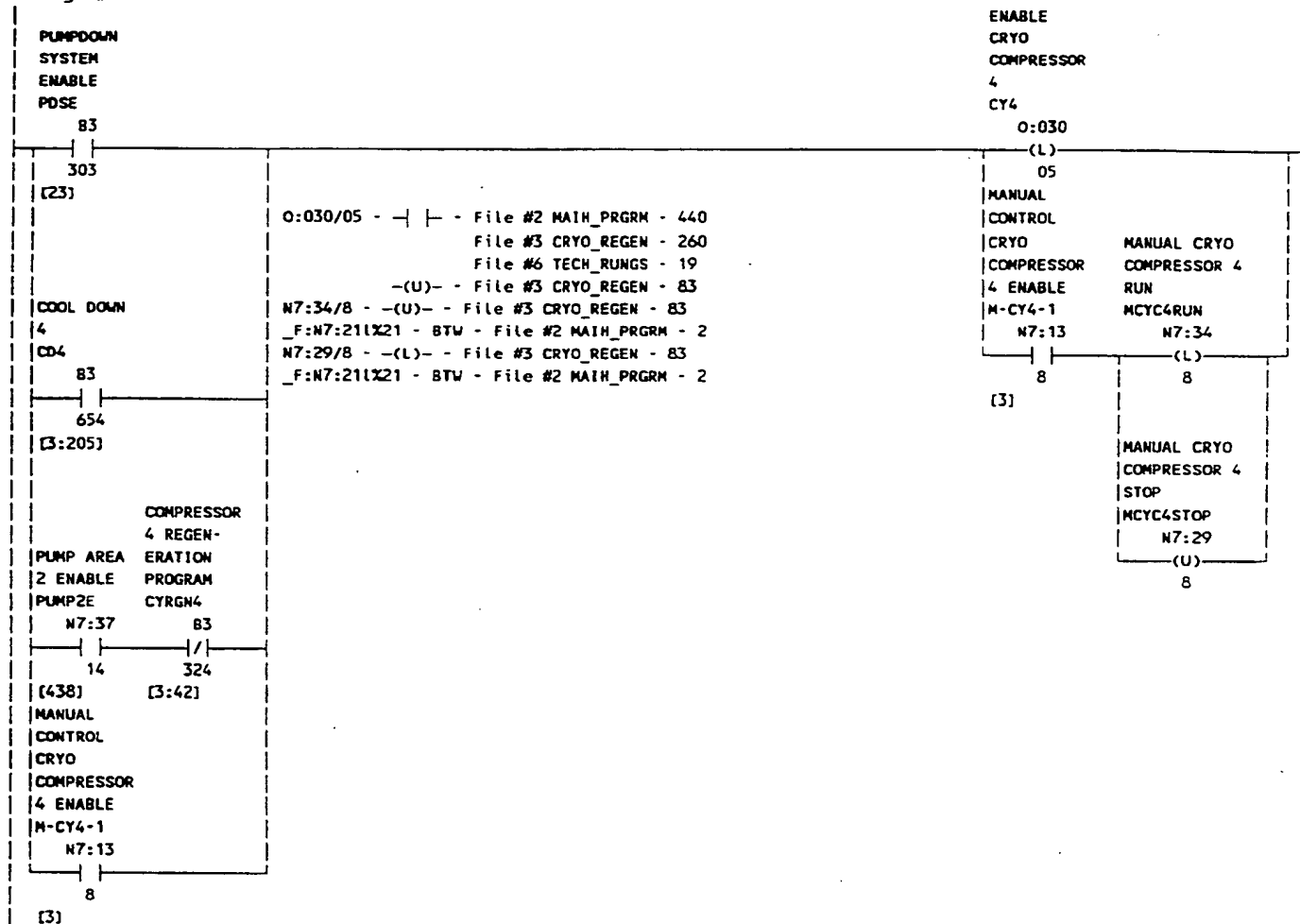
120

Rung #028



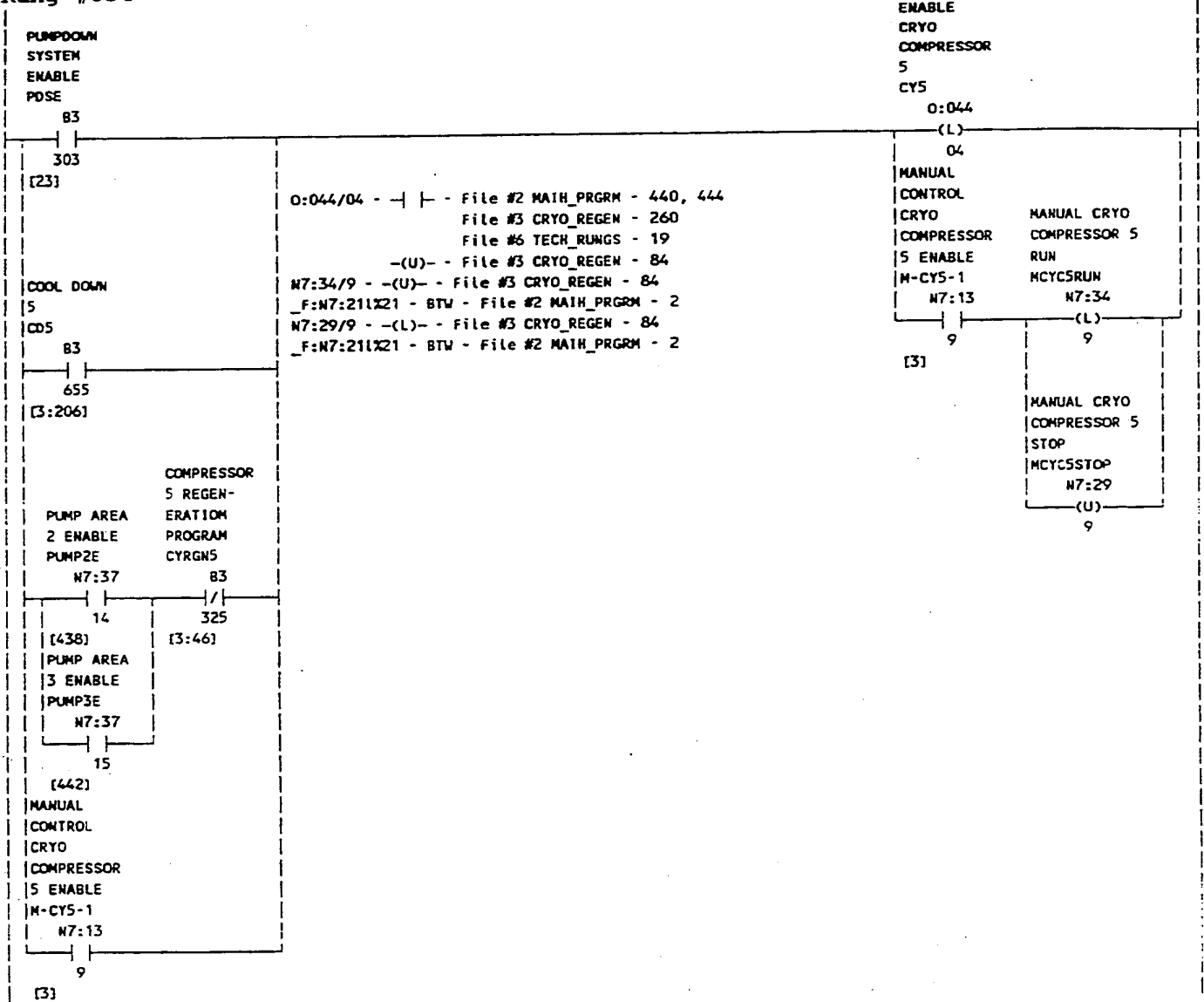
121

Rung #029



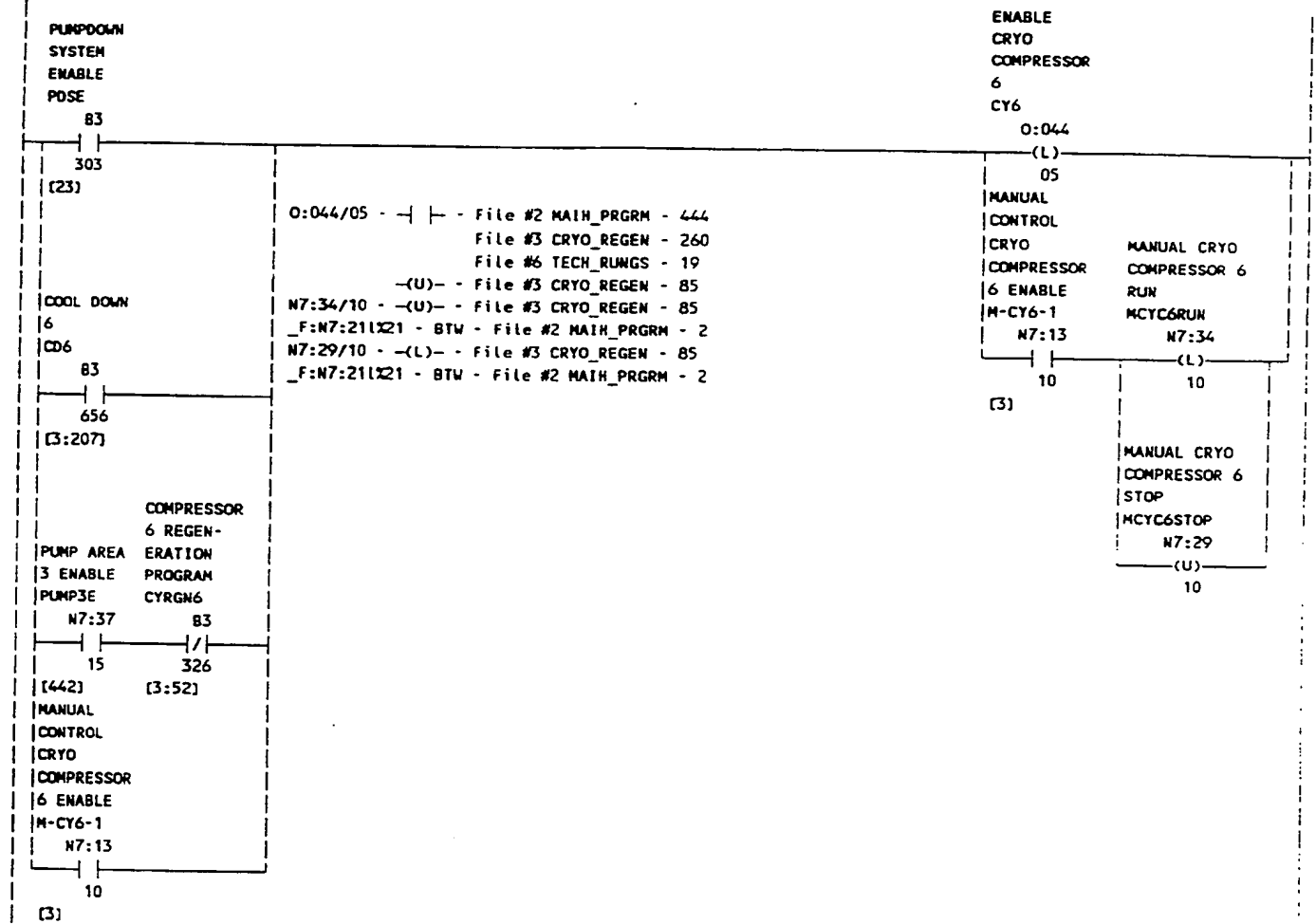
122

Rung #030



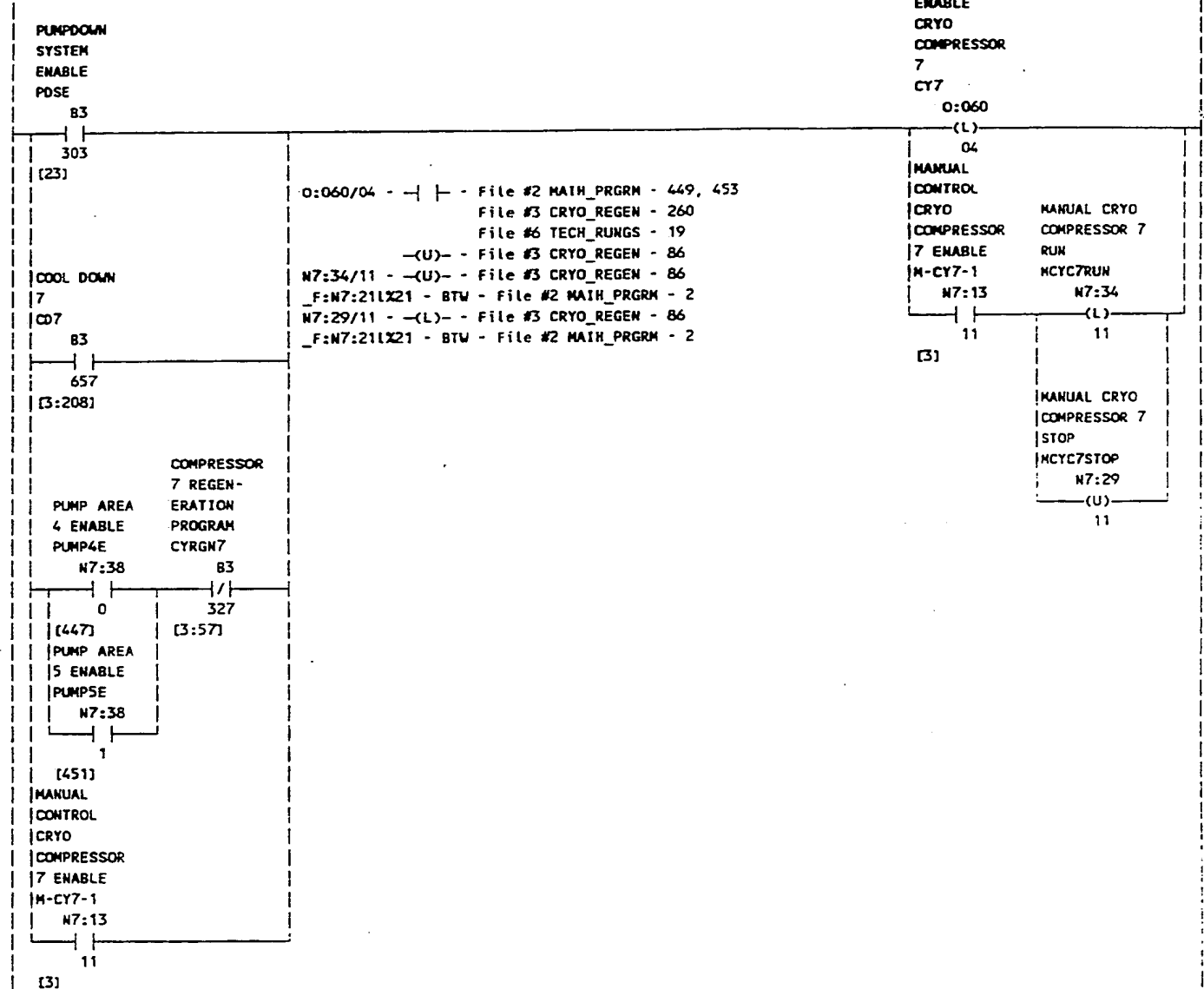
123

Rung #031



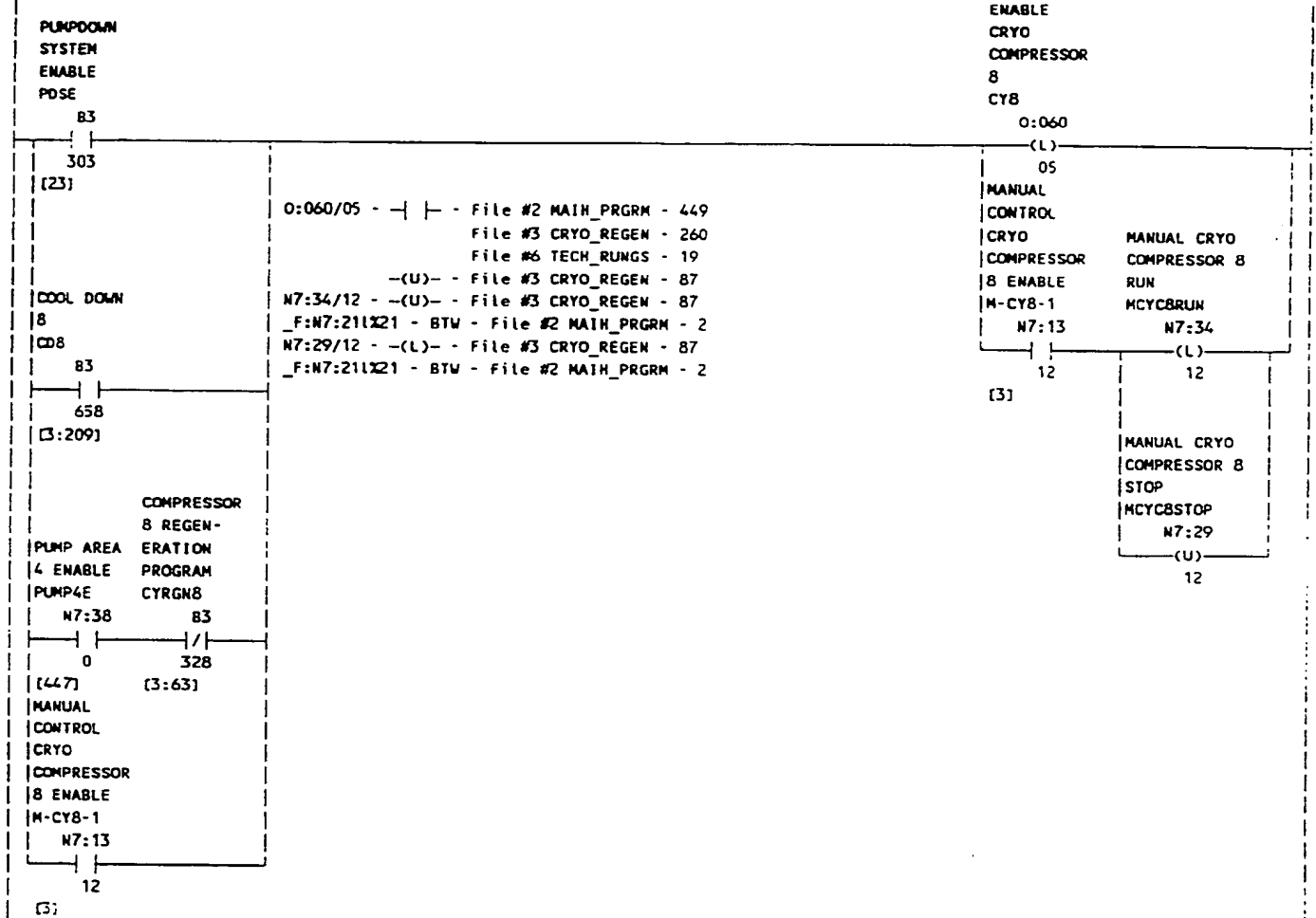
124

Rung #032



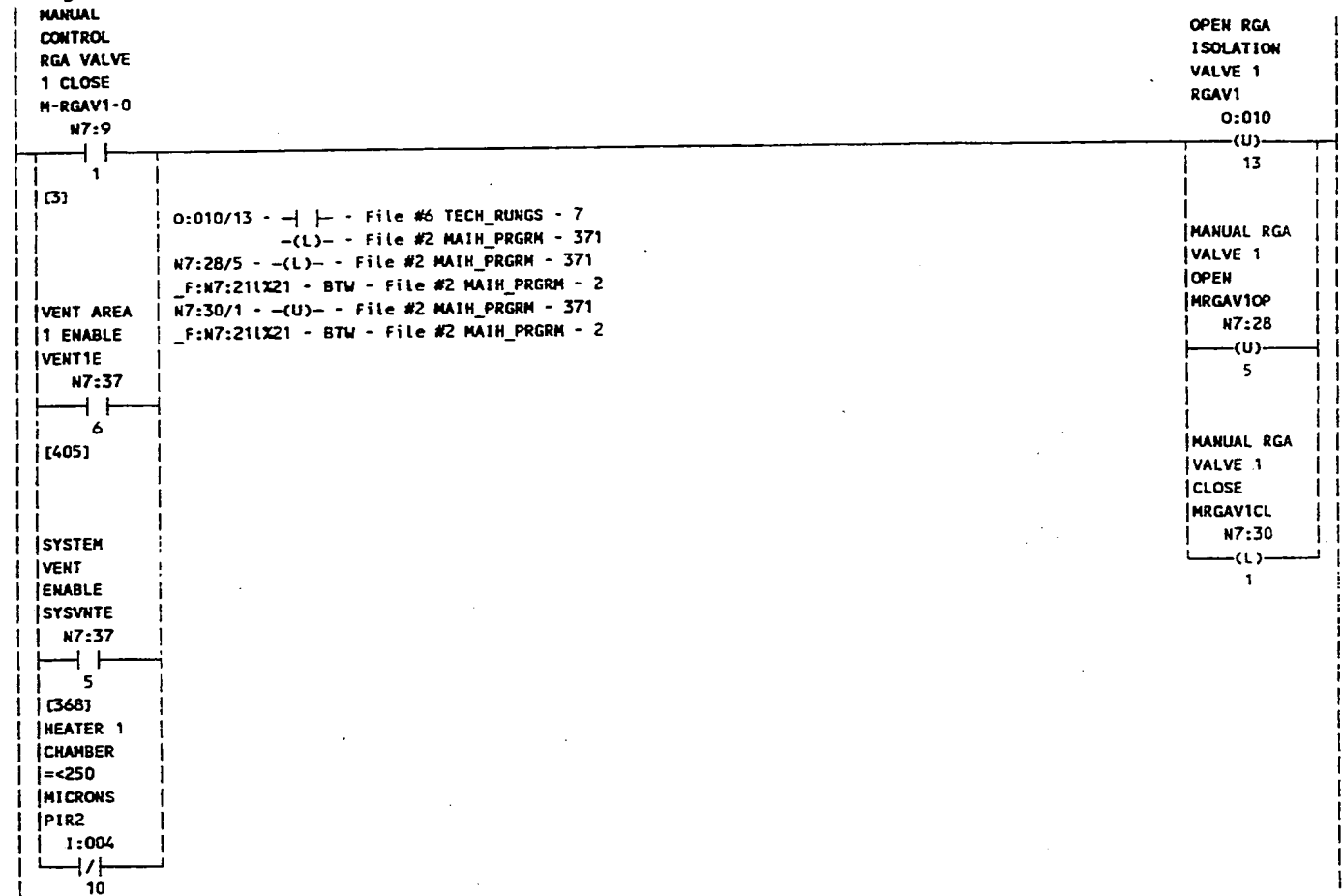
125

Rung #033



126

Rung #034



127

Rung #035

MANUAL
CONTROL
RGA VALVE
2 CLOSE
M-RGAV2-0
N7:9

OPEN RGA
ISOLATION
VALVE 2
RGAV2
0:030

2
[3]
VENT AREA
2 ENABLE
VENT2E
N7:37

```

O:030/13 - | | - File #6 TECH_RUNGS - 7
          -(L)- File #2 MATH_PRGRM - 372
N7:28/6 - -(L)- File #2 MATH_PRGRM - 372
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2
N7:30/2 - -(U)- File #2 MATH_PRGRM - 372
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

```

—(U)—

13

MANUAL RGA
VALVE 2
OPEN
MRGAVZOP
N7:28

- (U) -

6

[411]

SYSTEM
VENT
ENABLE
SYSVNT
#7:37

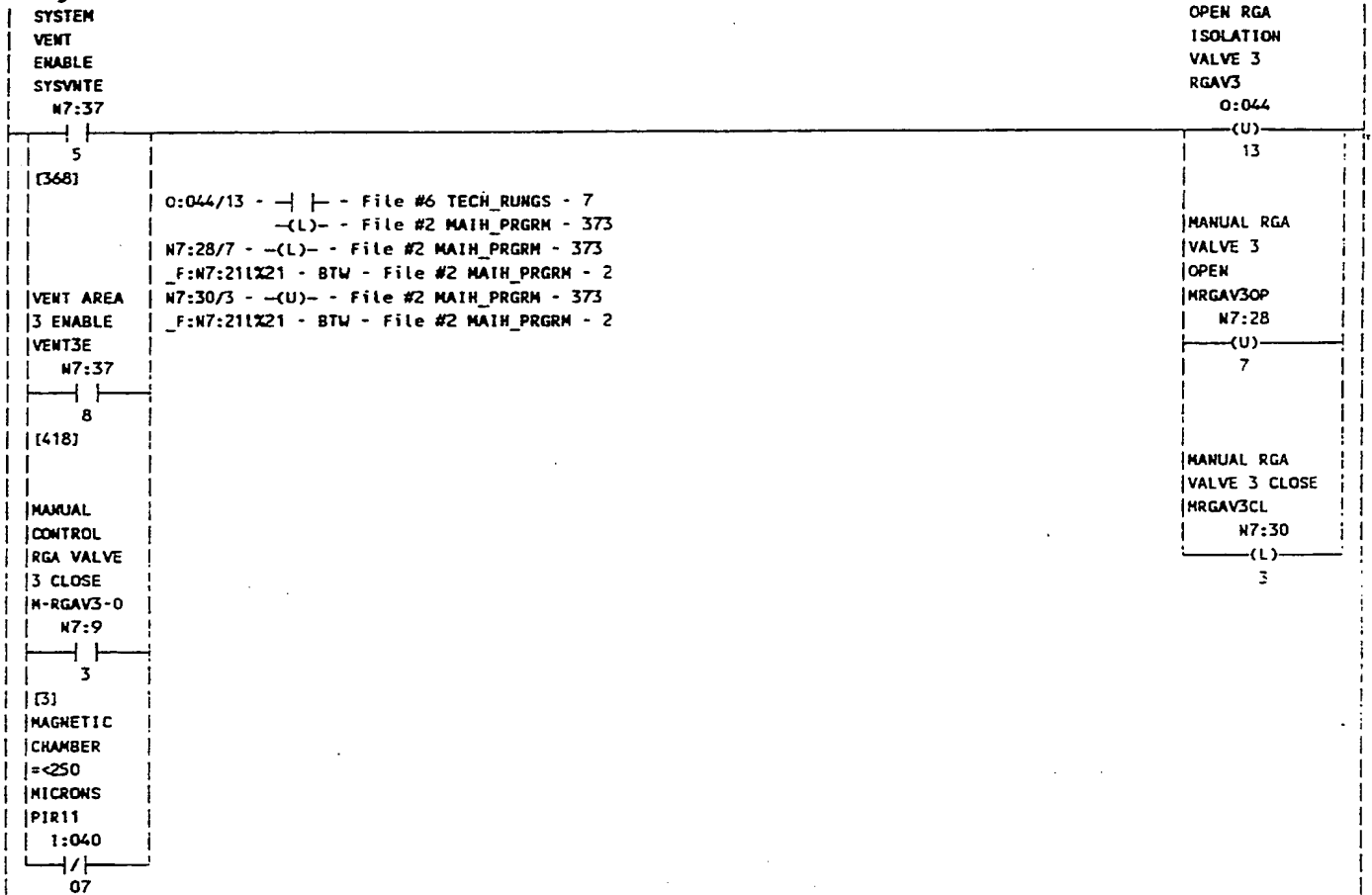
MANUAL RGA
VALVE 2 CLOSE
MRGAVZCL
N7:30

—(L

2

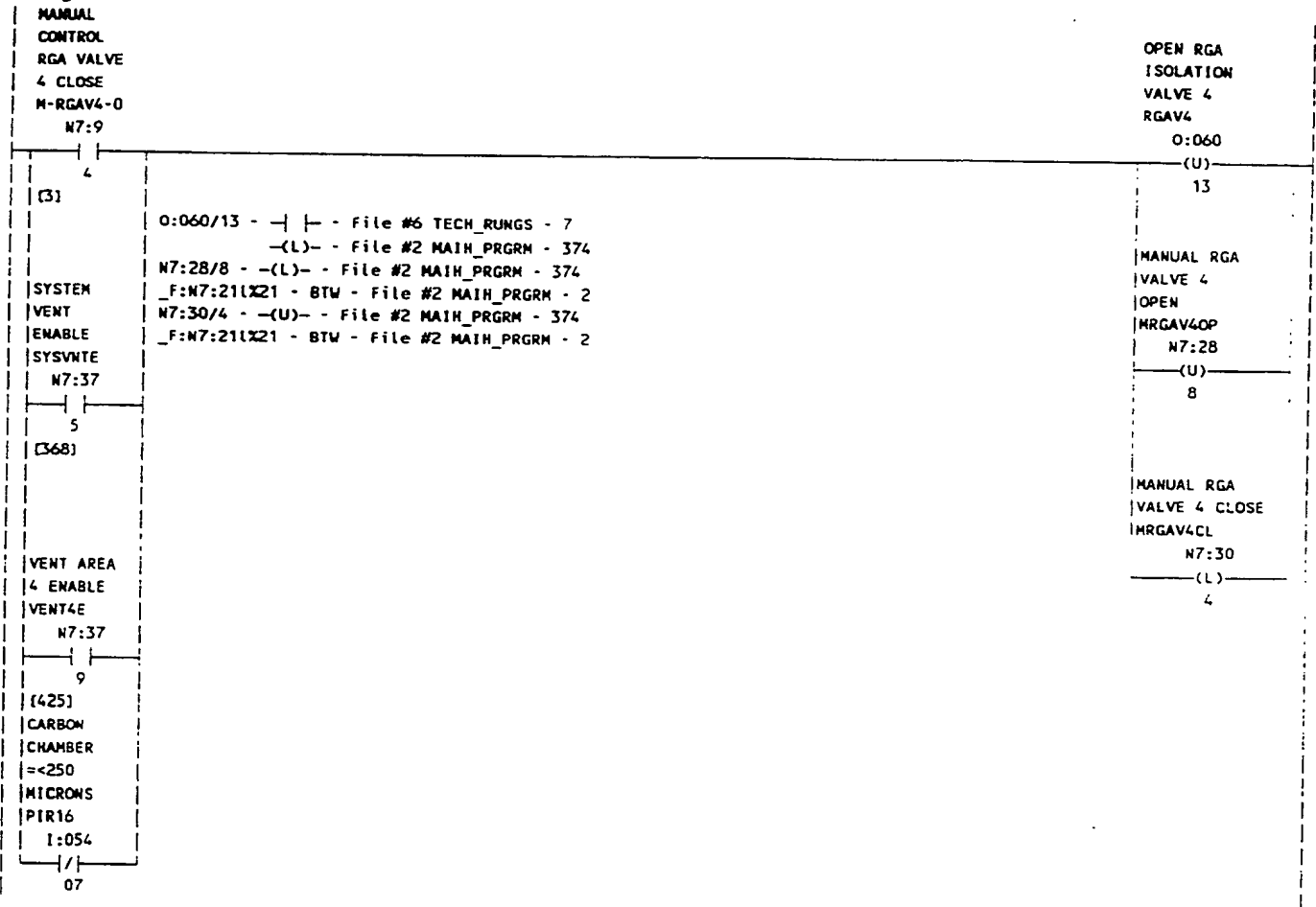
5
[368]
CHROME
CHAMBER
= < 250
MICRONS
PIR6
1:024
07

Rung #036



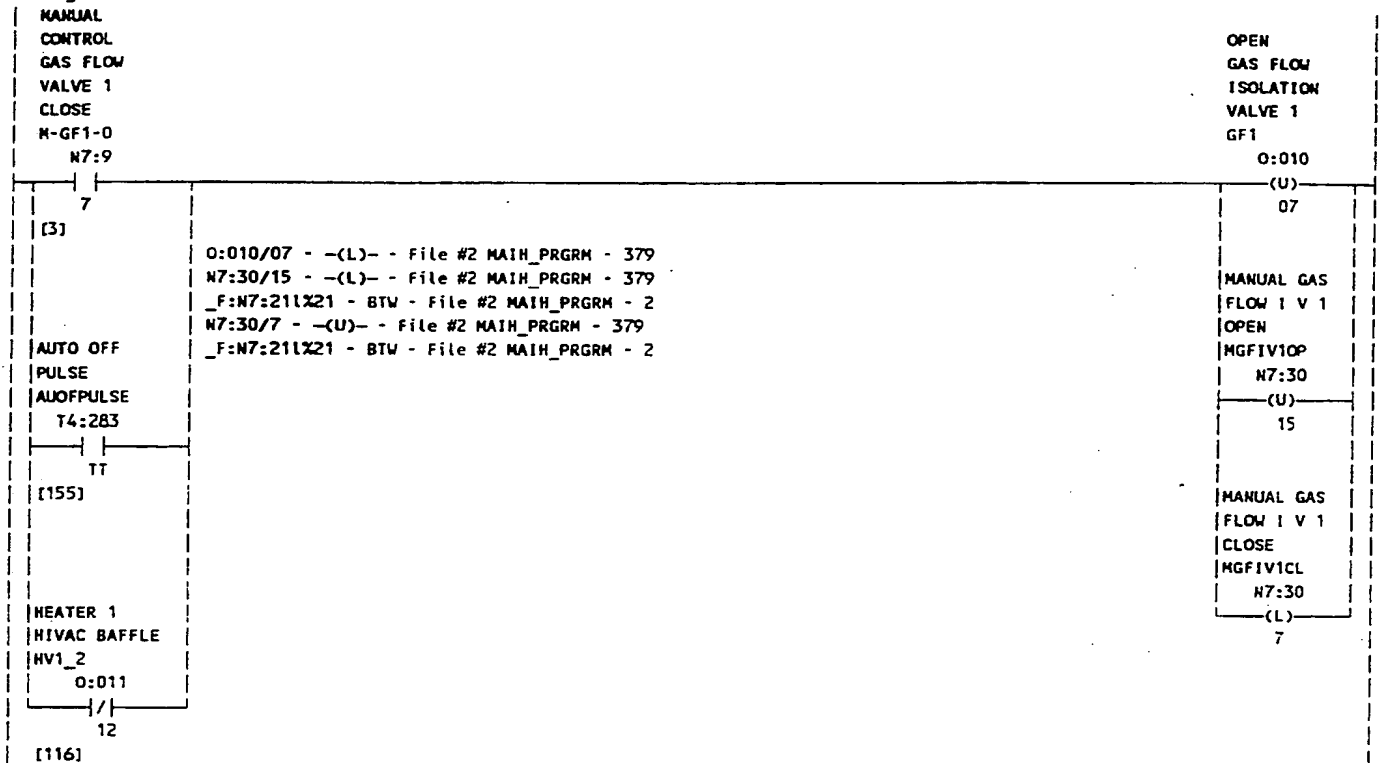
129

Rung #037

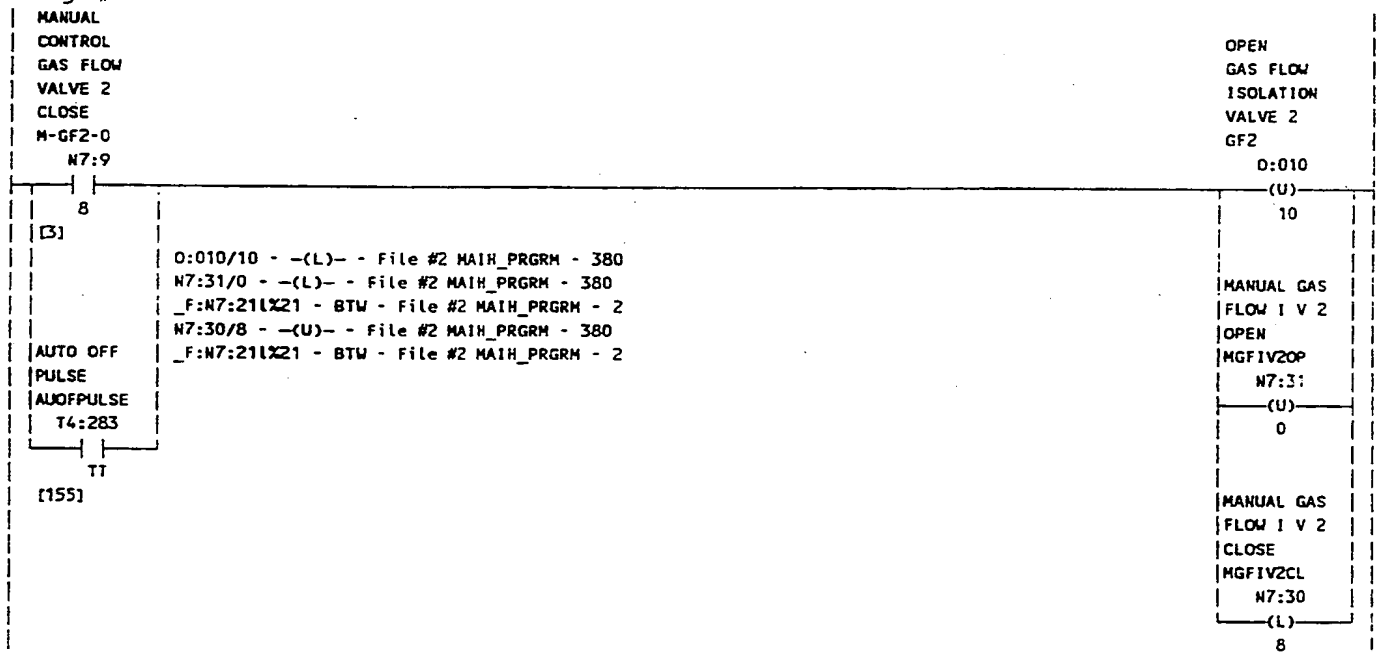


130

Rung #038

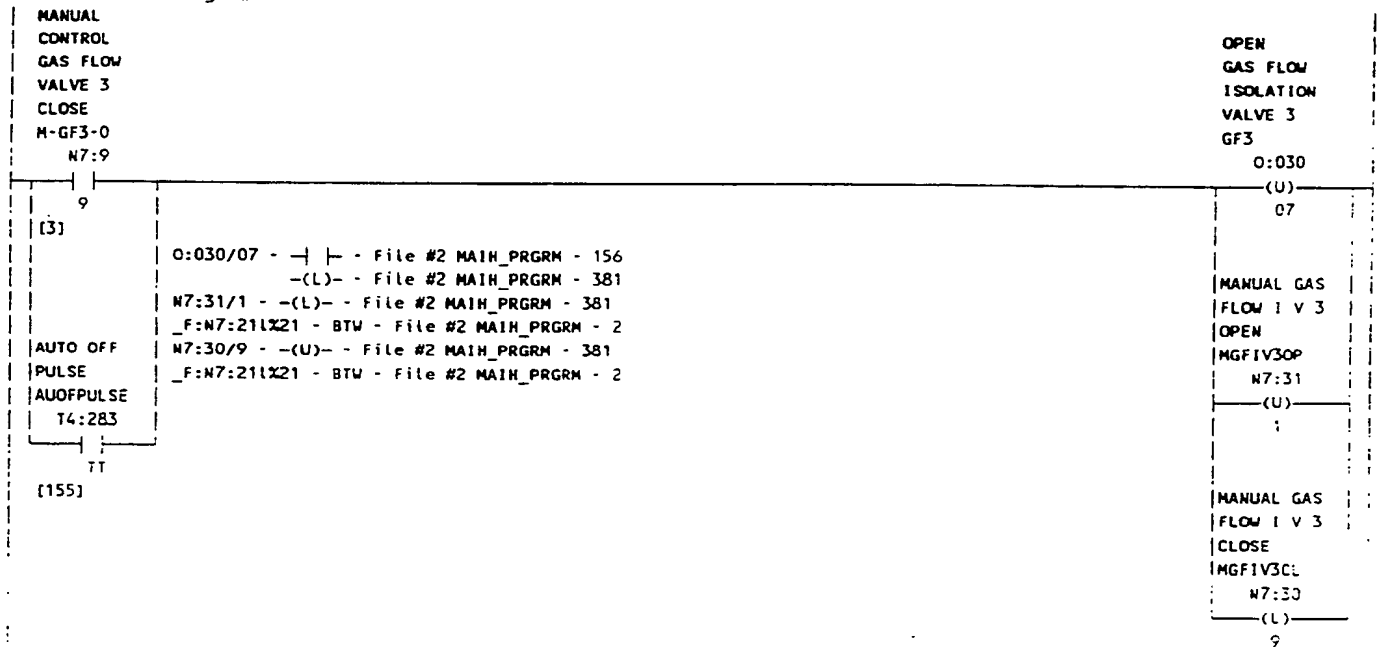


Rung #039



-131

BASE : Rung #040



132

Rung #041

MANUAL
CONTROL
GAS FLOW
VALVE 4
CLOSE
M-GH4-0
N7:9

OPEN
GAS FLOW
ISOLATION
VALVE 4
GF4

0:030

(U)

10

10

[3]

0:030/10 - -(L)- - File #2 MAIN_PRGRM - 382
N7:31/2 - -(L)- - File #2 MAIN_PRGRM - 382
_F:N7:21(X)21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/10 - -(U)- - File #2 MAIN_PRGRM - 382
_F:N7:21(X)21 - BTW - File #2 MAIN_PRGRM - 2

AUTO OFF
PULSE
AUOFFPULSE
T4:283

TT

[155]

MANUAL GAS
FLOW I V 4
OPEN
MGFIV4OP
N7:31

(U)

2

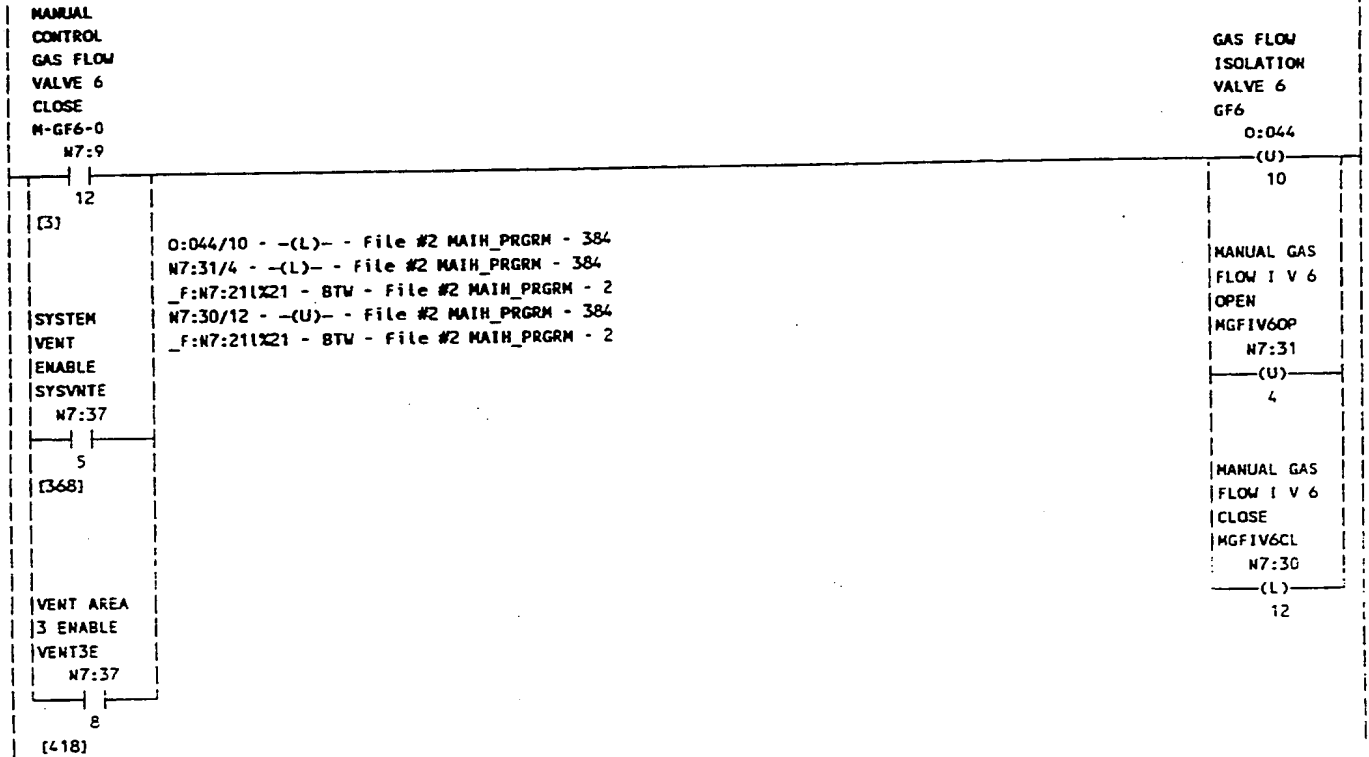
MANUAL GAS
FLOW I V 4
CLOSE
MGFIV4CL
N7:30

(L)

10

134

Rung #043



135

BASE : Rung #044

MANUAL
CONTROL
GAS FLOW
VALVE 7
CLOSE
M-GF7-0
N7:9

GAS FLOW
ISOLATION
VALVE 7
GF7
0:060

13
[3]

(U)
07

0:060/07 - (U) - File #2 MAIN_PRGRM - 156
-(L)- - File #2 MAIN_PRGRM - 385
N7:31/5 - -(L)- - File #2 MAIN_PRGRM - 385
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/13 - -(U)- - File #2 MAIN_PRGRM - 385
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

AUTO OFF
PULSE
AUOFFPULSE
T4:283

MANUAL GAS
FLOW I V 7
OPEN
MGFIV7OP
N7:31

(U)
5

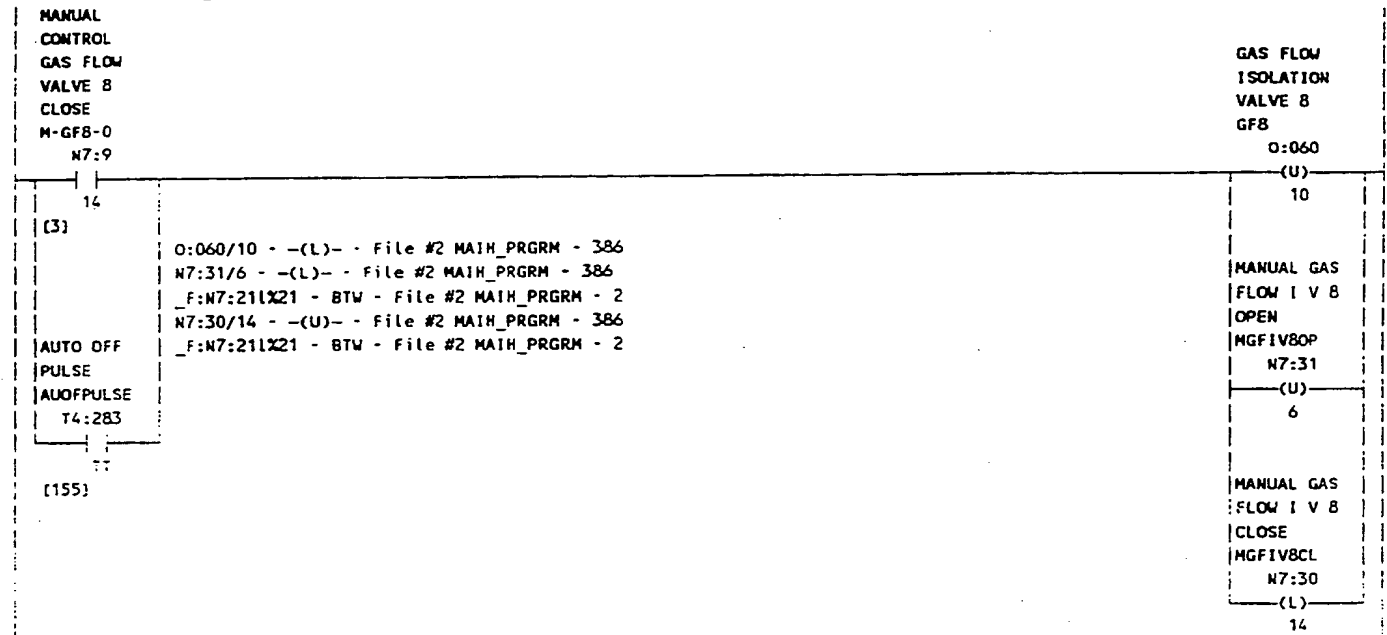
TT

[155]

MANUAL GAS
FLOW I V 7
CLOSE
MGFIV7CL
N7:30
(L)
13

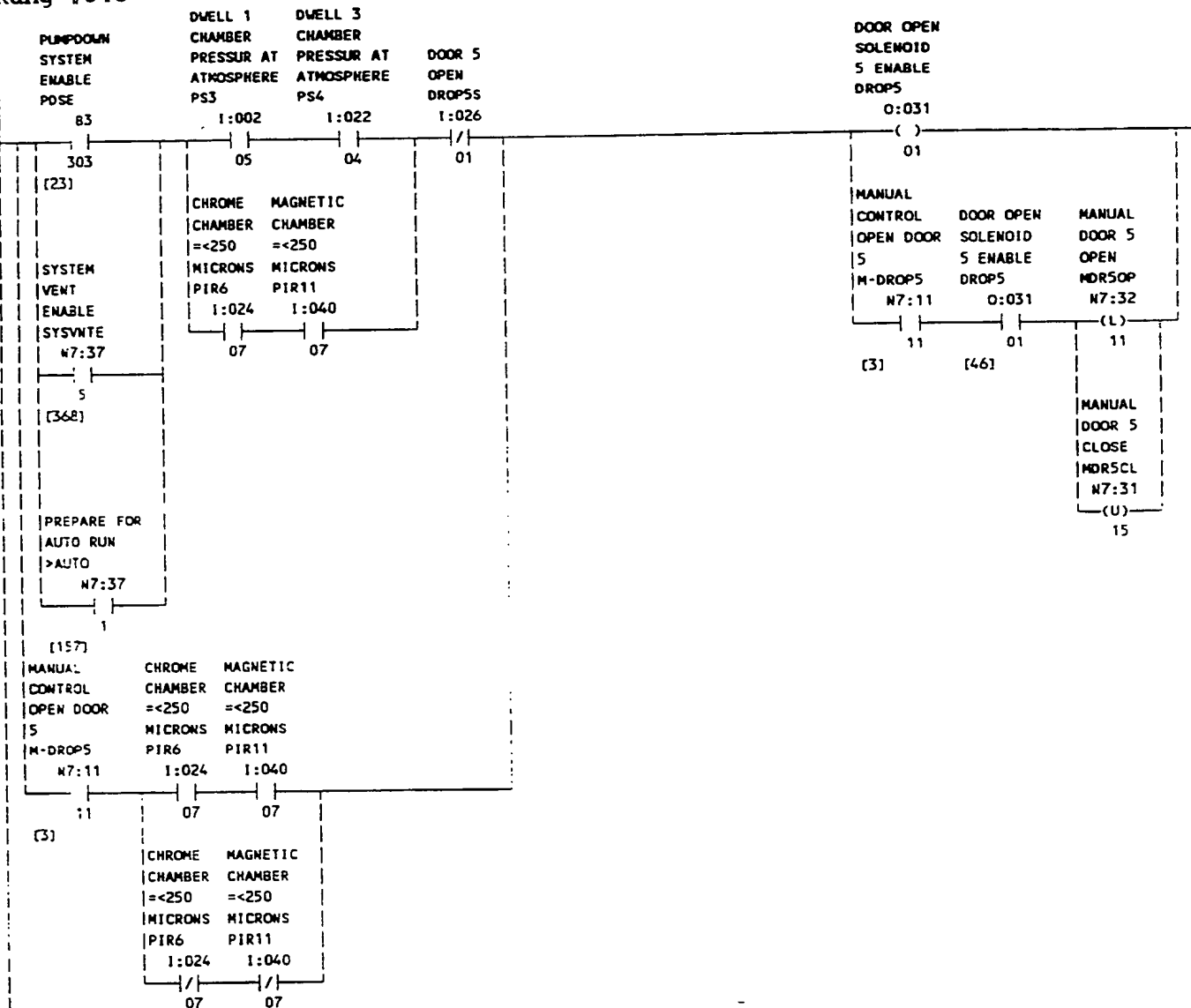
136

BASE : Rung #045



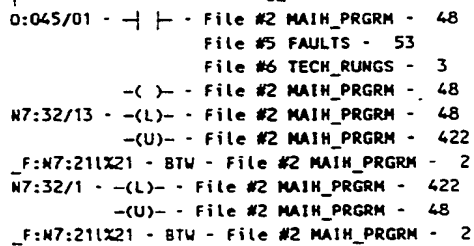
137

Rung #046



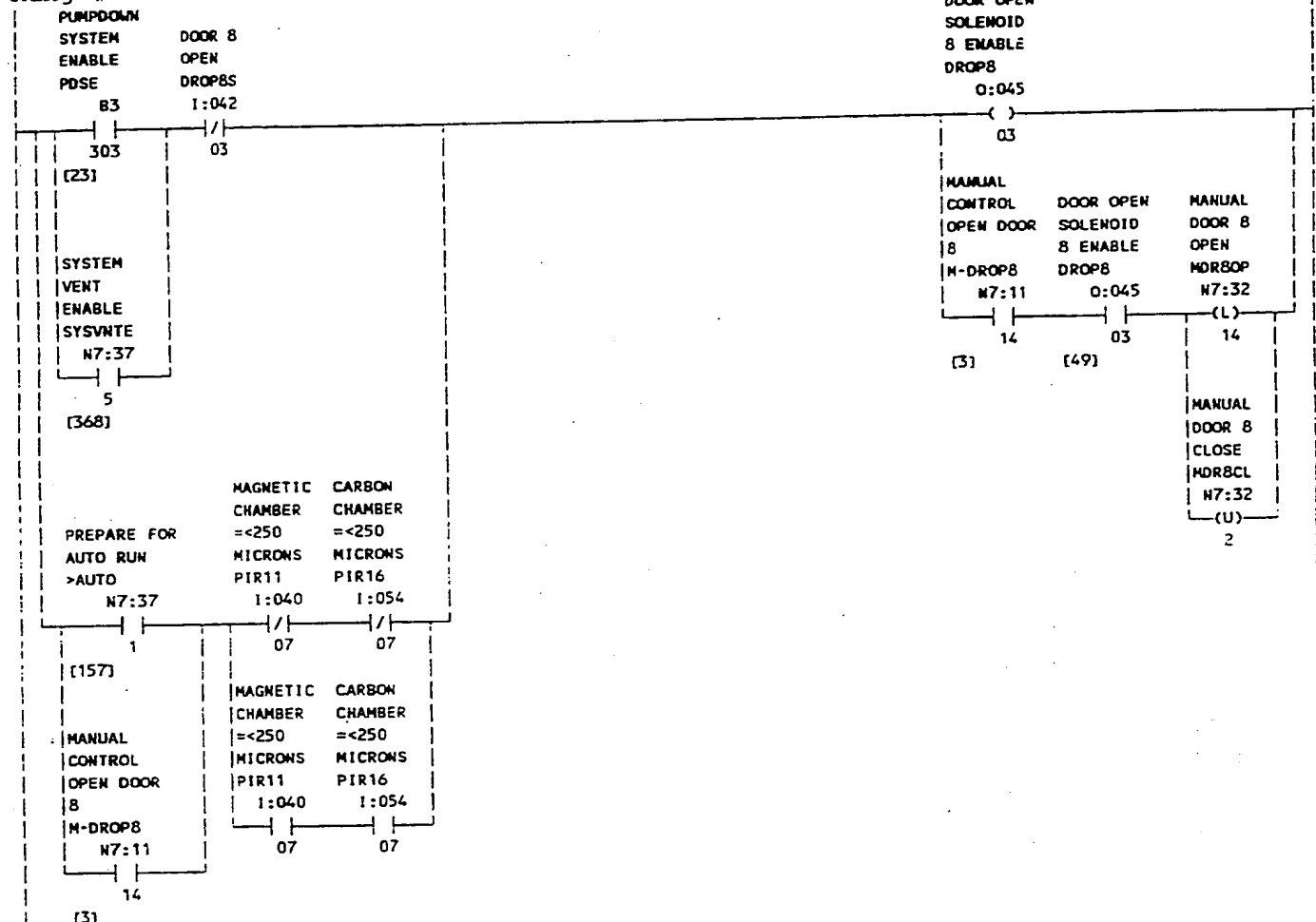
0:031/01 - | - File #2 MAIH_PRGRM - 46
 File #5 FAULTS - 49
 File #6 TECH_RUNGS - 2
 -() - File #2 MAIH_PRGRM - 46
 N7:32/11 - -(L)- File #2 MAIH_PRGRM - 46
 -(U)- File #2 MAIH_PRGRM - 414
 _F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
 N7:31/15 - -(L)- File #2 MAIH_PRGRM - 414
 -(U)- File #2 MAIH_PRGRM - 46
 _F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2

Rung #048



140

Rung #049



```

0:045/03 - | | - File #2 MAIN_PRGRM - 49
          File #5 FAULTS - 55
          File #6 TECH_RUNGS - 3
          -( ) - File #2 MAIN_PRGRM - 49
W7:32/14 - -(L)- File #2 MAIN_PRGRM - 49
          -(U)- File #2 MAIN_PRGRM - 427
_F:W7:211X21 - BTW - File #2 MAIN_PRGRM - 2
W7:32/2 - -(L)- File #2 MAIN_PRGRM - 427
          -(U)- File #2 MAIN_PRGRM - 49
F:W7:211X21 - BTW - File #2 MAIN_PRGRM - 2

```

141

Rung #050

DWELL 1
CHAMBER
PRESSUR AT
ATMOSPHERE
PS3

1:002

05

T4:318.DW - | - File #2 MAIN_PRGRM - 51

CHAMBER VENT 2
CLOSE DELAY
CV2_DLY

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:318
BASE (SEC):	1.0 (DN)
PRESET:	2
ACCUM:	0

142

Rung #051

OPEN
DWEELL 2
VENT VALVE
CV2

0:007

(U)

17

CV2_DLY
T4:318

DN

[50]

MANUAL
CONTROL
CHAMBER
VENT VALVE
CLOSE
M-CV2-0

N7:4

1

[3]

HEATER 2
CHAMBER
GATE VALVE DOOR 4
CLOSE CLOSED
HV2S1 DRCL4S

1:004

1:006

/

/

00

06

DWEELL 1
CHAMBER
GATE VALVE
CLOSED
HV3S1

1:004

/

03

DWEELL 2
CHAMBER
GATE VALVE
CLOSED
HV4S1

1:022

/

06

HEATER 3
CHAMBER
GATE VALVE
CLOSED
HV5S1

1:024

/

00

ABORT SYSTEM
VENT
BORT_SYS_VNT
N7:17

10

[3]

0:007/17 - | | - File #5 FAULTS - 144
File #6 TECH_RUNGS - 0
- | | - File #2 MAIN_PRGRM - 368
File #5 FAULTS - 146
-(L)- - File #2 MAIN_PRGRM - 396

143

Rung #052

DWELL 3
CHAMBER
PRESSUR AT
ATMOSPHERE
PS4

1:022

04

T4:319.DN - | - File #2 MATH_PRGRM - 53

CHAMBER VENT 3
CLOSE DELAY
CV3_DLY

TON

TIMER ON DELAY	(EN)
TIMER: T4:319	
BASE (SEC): 1.0	(DN)
PRESET: 2	
ACCUM: 0	

144

Rung #053

OPEN
DWELL 3
VENT VALVE
CV3

0:027

(U)

16

CV3_DLY
T4:319

DN

[52]

MANUAL
CONTROL
CHAMBER
VENT VALVE
CLOSE
M-CV3-0

N7:4

2

[3]

HEATER 3
CHAMBER
DOOR 6 GATE VALVE
CLOSED CLOSED
DRCL6S HV5S1

I:026 I:024

02

00

DWELL 3
CHAMBER
GATE VALVE
CLOSED
HV6S1

I:024

03

DWELL 4
CHAMBER
GATE VALVE
CLOSED
HV7S1

I:036

06

BUFFER 3
CHAMBER
GATE VALVE
CLOSED
HV8S1

I:040

00

ABORT SYSTEM
VENT
BORT_SYS_VNT
N7:17

10

[3]

0:027/16 - | | - File #5 FAULTS - 148
File #6 TECH_RUNGS - 0
-|/| - File #2 MATH_PRGRM - 368
File #5 FAULTS - 150
-(L)- - File #2 MATH_PRGRM - 401

145

Rung #054

DWELL 5

CHAMBER

PRESSUR AT

ATMOSPHERE

PS5

1:036

04

T4:320.DW - - File #2 MAIN_PRGRM - 55

CHAMBER VENT 4

CLOSE DELAY

CV4_DLY

TON

TIMER ON DELAY (EN)

TIMER: T4:320

BASE (SEC): 1.0 (DN)

PRESET: 2

ACCUM: 0

146

Rung #055

OPEN
DWELL 5
VENT VALVE
CV4

0:043

(U)

16

CV4_DLY
T4:320

DM

[54]

MANUAL
CONTROL
CHAMBER
VENT VALVE
4 CLOSE
M-CV4-0

N7:4

3

[3]

BUFFER 3
CHAMBER
GATE VALVE DOOR 8
CLOSED CLOSED
HV8S1 DRCL8S
1:040 1:042

00

02

DWELL 5

CHAMBER
GATE VALVE
CLOSED
HV9S1

1:040

03

DWELL 6

CHAMBER
GATE VALVE
CLOSED
HV10S1

1:052

06

BUFFER 4

CHAMBER
GATE VALVE
CLOSED
HV11S1

1:054

00

ABORT SYSTEM

VENT

BORT_SYS_VNT

N7:17

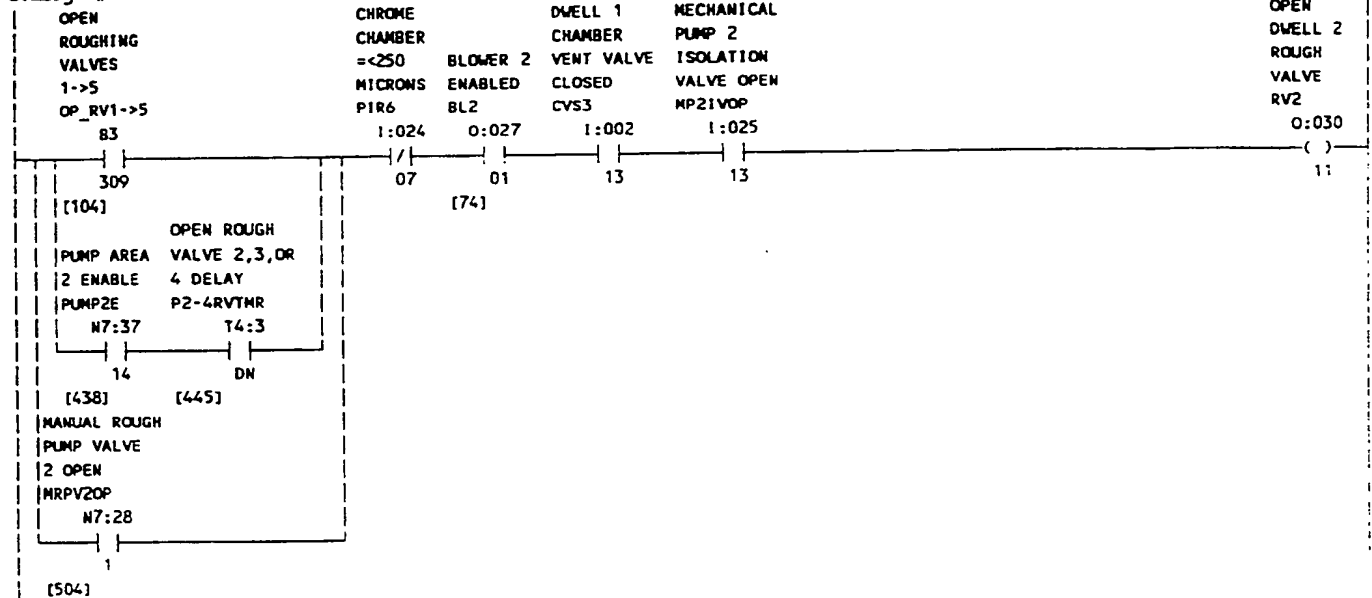
10

[3]

0:043/16 - | | - File #5 FAULTS - 152
File #6 TECH_RUNGS - 0
-|/| - File #2 MATH_PRGRM - 368
File #5 FAULTS - 154
-(L)- - File #2 MATH_PRGRM - 403

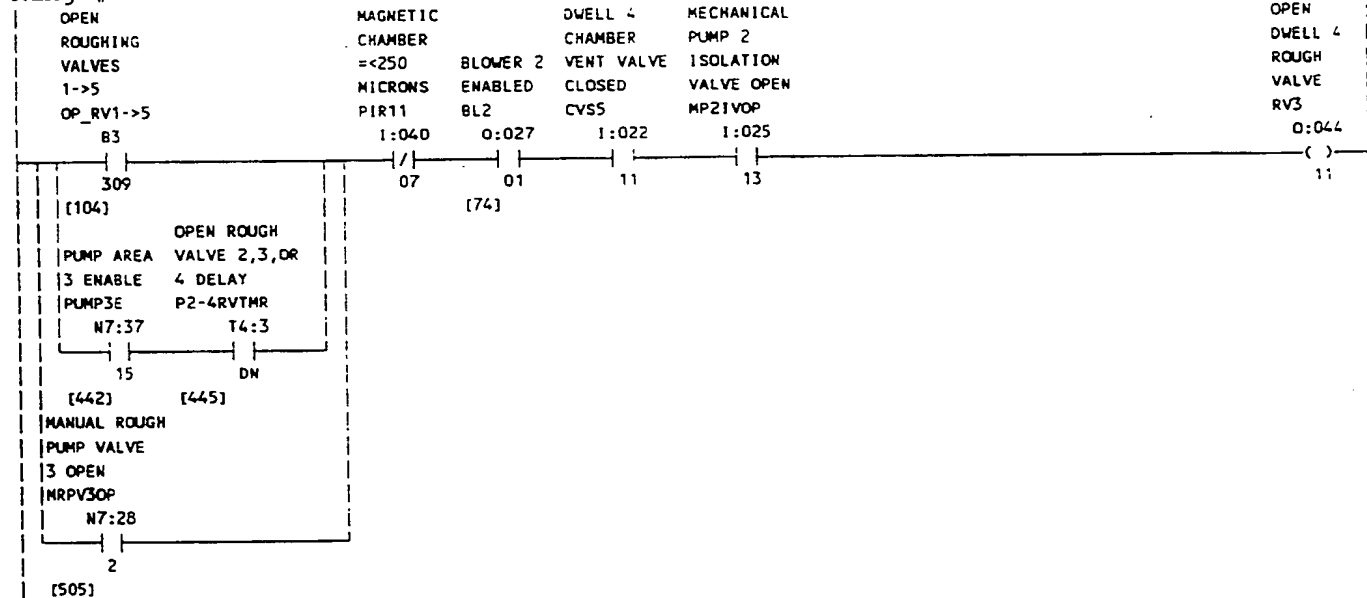
147

Rung #056



0:030/11 - | | - File #5 FAULTS - 163
 File #6 TECH_RUNGS - 0
 -|/| - File #5 FAULTS - 165
 -() - File #2 MAIN_PRGRM - 56

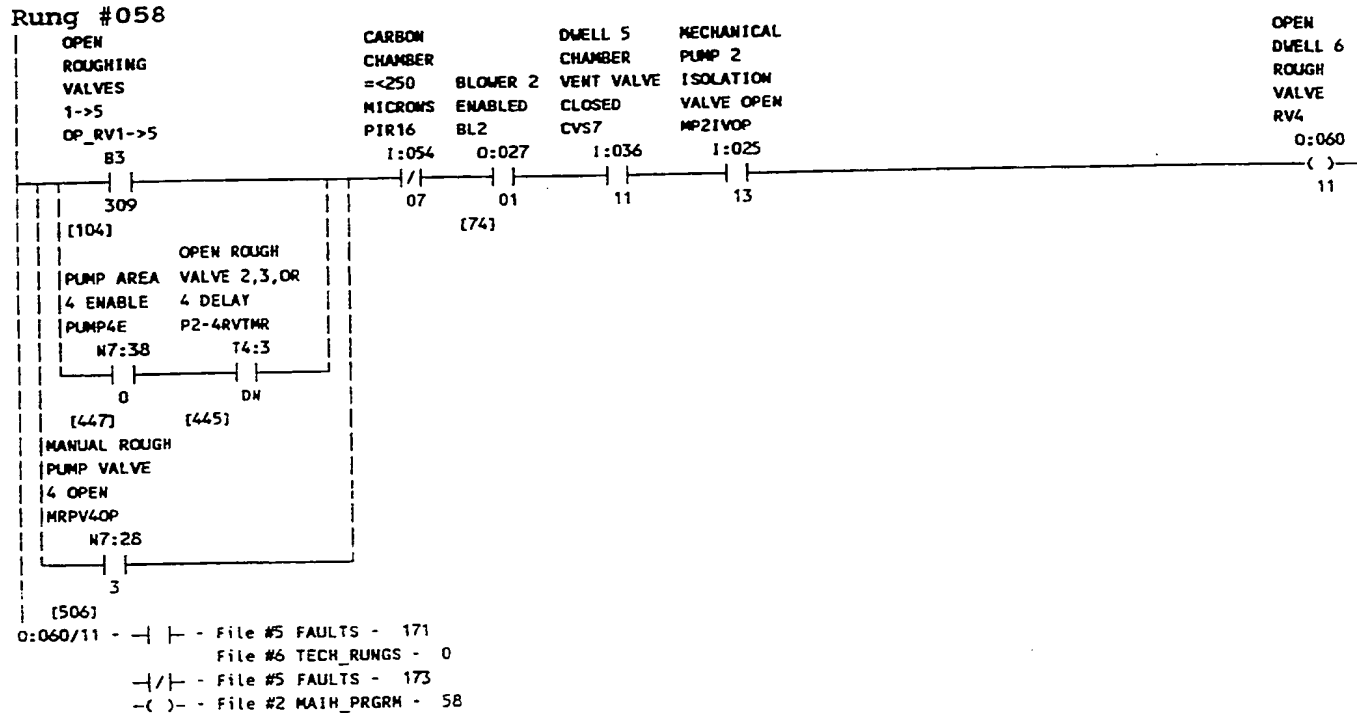
Rung #057



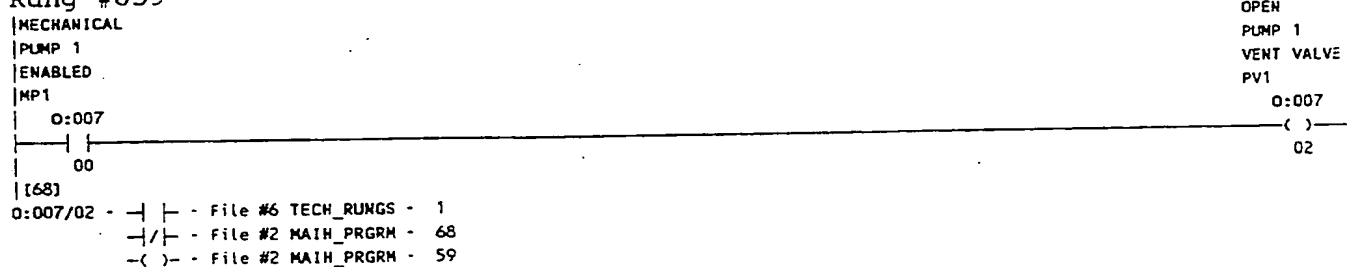
0:044/11 - | | - File #5 FAULTS - 167
 File #6 TECH_RUNGS - 0
 -|/| - File #5 FAULTS - 169
 -() - File #2 MAIN_PRGRM - 57

148

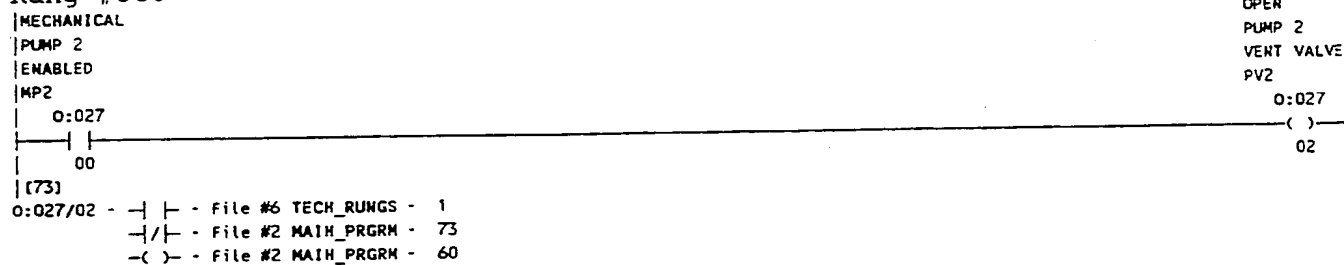
Rung #058



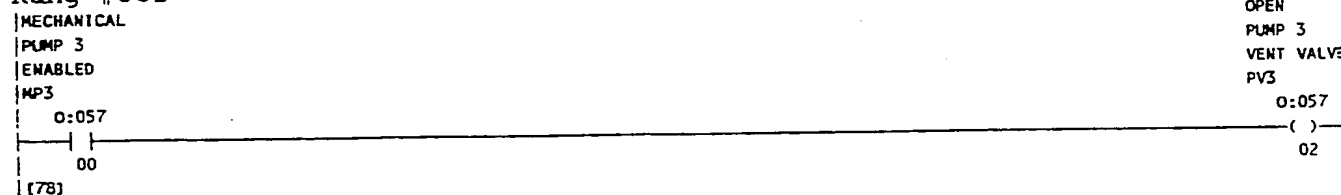
Rung #059



Rung #060



Rung #061



149

0:057/02 - | | - File #6 TECH_RUNGS 1
 - | | - File #2 MAIN_PRGRM - 78
 - () - File #2 MAIN_PRGRM - 61

Rung #062

DOOR 1	DOOR 1	DOOR 12	DOOR 12	DOOR 1&12
CLOSED	OPEN	CLOSED	OPEN	CLOSED
DRCL1S	DROP1S	DRCL12S	DROP12S	DR1&12CL
I:006	I:006	I:056	I:056	B3
				()
00	01	06	07	304

B3/304 - | | - File #2 MAIN_PRGRM - 68
 - () - File #2 MAIN_PRGRM - 62

Rung #063

		RGA 2	RGA 2	RGA 3	RGA 3	RGA 4	RGA 4	ALL RGA
		ISOLATION	ISOLATION	ISOLATION	ISOLATION	ISOLATION	ISOLATION	ISOLATION
RGA VALVE	RGA VALVE	VALVE	VALVE	VALVE	VALVE	VALVE	VALVE	VALVES
SENSOR CLOSED	SENSOR OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED
RGAS1	RGAS2	RGAS3	RGAS4	RGAS5	RGAS6	RGAS7	RGAS8	RGACL
I:005	I:005	I:025	I:025	I:041	I:041	I:055	I:055	B3
								()
16	17	16	17	16	17	16	17	305

B3/305 - | | - File #2 MAIN_PRGRM - 68,391
 - () - File #2 MAIN_PRGRM - 63

Rung #064

DOOR 3	DOOR 3	DOOR 4	DOOR 4	DOOR 5	DOOR 5	DOOR 6	DOOR 6	DOORS 2->6
CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	OPEN
DRCL3S	DROP3S	DRCL4S	DROP4S	DRCL5S	DROP5S	DRCL6S	DROP6S	DR2->6OP
I:006	I:006	I:006	I:006	I:026	I:026	I:026	I:026	B3
								()
04	05	06	07	00	01	02	03	306

B3/306 - | | - File #2 MAIN_PRGRM - 68,391
 - () - File #2 MAIN_PRGRM - 64

Rung #065

DOOR 7	DOOR 7	DOOR 8	DOOR 8	DOOR 9	DOOR 9	DOOR 10	DOOR 10	DOORS 7->11
CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	OPEN
DRCL7S	DROP7S	DRCL8S	DROP8S	DRCL9S	DROP9S	DRCL10S	DROP10S	DR7->11OP
I:042	I:042	I:042	I:042	I:056	I:056	I:056	I:056	B3
								()
00	01	02	03	00	01	02	03	307

B3/307 - | | - File #2 MAIN_PRGRM - 68,391
 - () - File #2 MAIN_PRGRM - 65

Rung #066

LLOCK	LLOCK	DWELL 2	DWELL 2	DWELL 4	DWELL 4	DWELL 5	DWELL 5	EXLOCK	EXLOCK	
CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	
ROUGH	ROUGH	ROUGH	ROUGH	ROUGH	ROUGH	ROUGH	ROUGH	ROUGH	ROUGH	ROUGH
VALVE	VALVE	VALVE RV2	VALVE	VALVE	VALVE	VALVE	VALVE	VALVE	VALVE	VALVES
CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	CLOSED
RVS1	RVS2	RVS3	RVS4	RVS5	RVS6	RVS7	RVS8	RVS9	RVS10	RVCL
I:002	I:002	I:022	I:022	I:036	I:036	I:052	I:052	I:052	I:052	B3
										()
15	16	15	16	15	16	14	15	16	17	310

B3/310 - | | - File #2 MAIN_PRGRM - 68,391
 - () - File #2 MAIN_PRGRM - 66

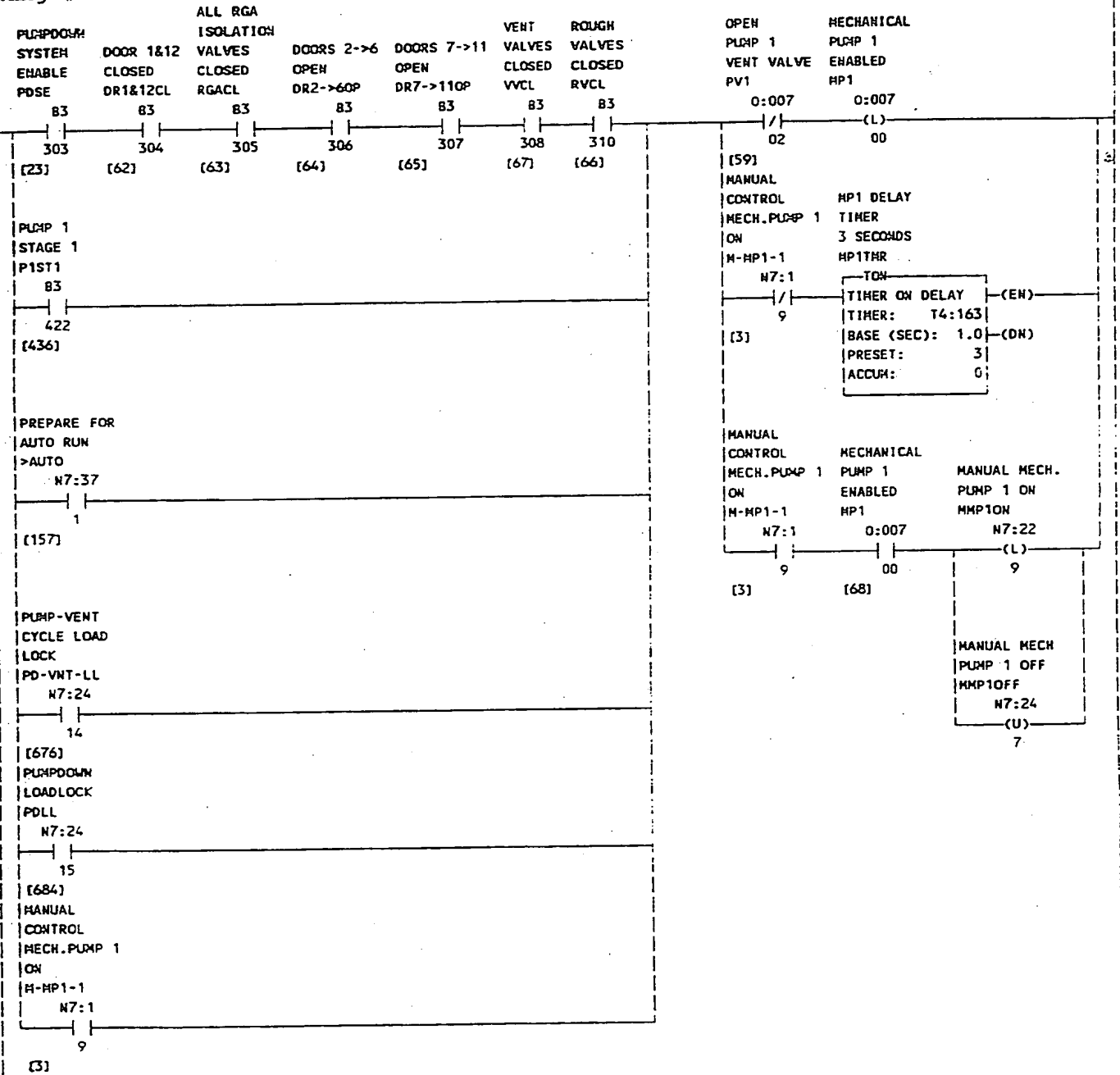
Rung #067

OPEN	DWELL 1	DWELL 1	DWELL 4	DWELL 3	DWELL 5	DWELL 5	OPEN	
LOAD LOCK	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	EXLOCK	VENT
CHAMBER	VENT VALVE	VENT VALVE	VENT VALVE	VENT VALVE	VENT VALVE	VENT VALVE	CHAMBER	VALVES
VENT VALVE	CLOSED	OPEN	CLOSED	OPEN	CLOSED	OPEN	VENT VALVE	CLOSED
CV1	CVS3	CVS4	CVS5	CVS6	CVS7	CVS8	CV5	WVCL
0:007	I:002	I:002	I:022	I:022	I:036	I:036	0:057	B3
								()
16	13	14	11	12	11	12	16	308

[173] [346]

150

83/308 - | | - File #2 MAIN_PRGRM -
 - () - File #2 MAIN_PRGRM - 67
 Rung #068

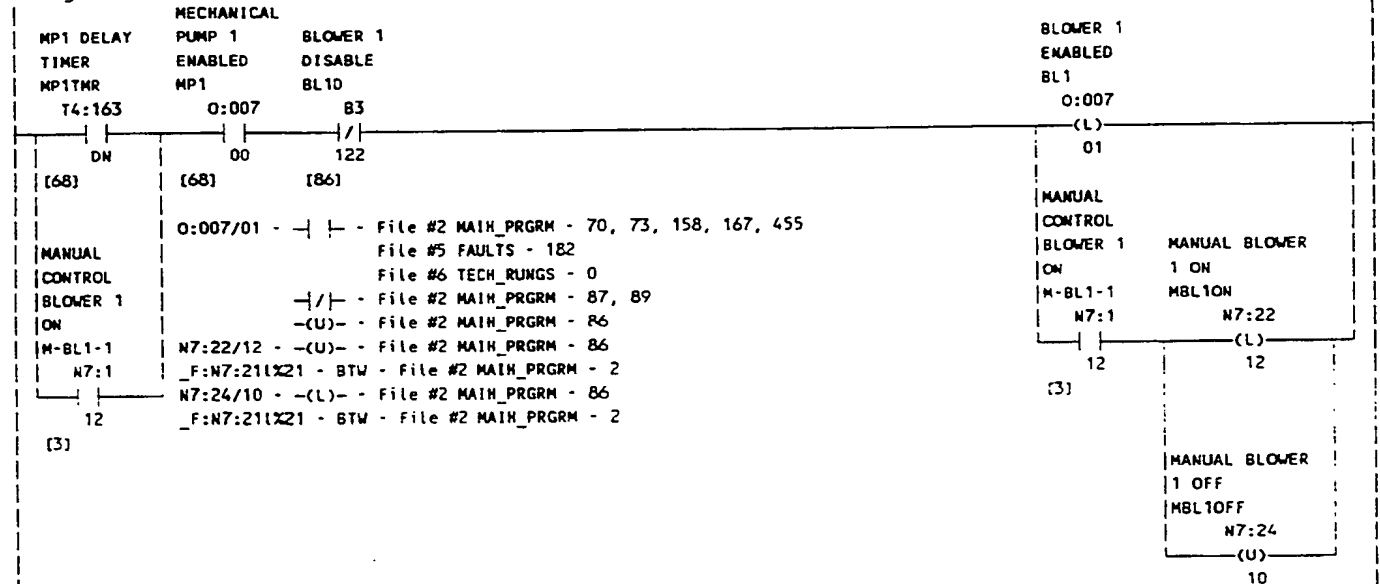


0:007/00 - | | - File #2 MAIN_PRGRM - 59,69,158
 File #5 FAULTS - 182
 File #6 TECH_RUNGS - 0
 -(L)- - File #2 MAIN_PRGRM - 68

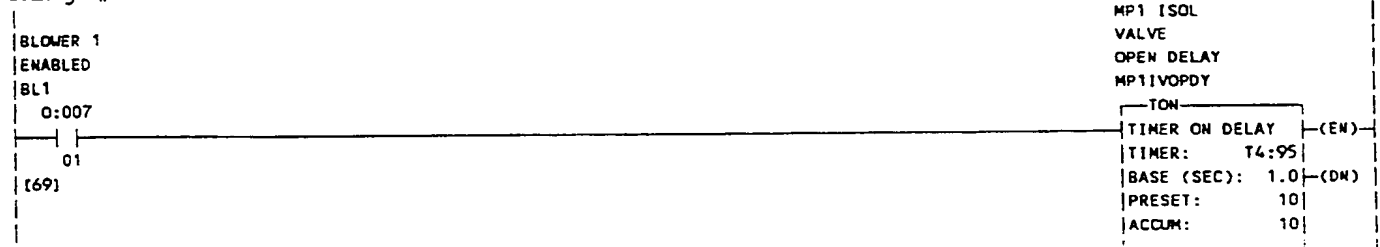
151

-(U)- - File #2 MAIN_PRGRM - 89
 T4:163.DN - | | - File #2 MAIN_PRGRM - 69,73,78
 N7:22/9 - -(L)- - File #2 MAIN_PRGRM - 68
 -(U)- - File #2 MAIN_PRGRM - 89
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:24/7 - -(L)- - File #2 MAIN_PRGRM - 89
 -(U)- - File #2 MAIN_PRGRM - 68
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #069



Rung #070



T4:95.TT - | | - File #2 MAIN_PRGRM - 71

Rung #071



T4:5.TT - | | - File #2 MAIN_PRGRM - 72

152

Rung #072

BL10LY

T4:5

TT

(71)

0:010/03 - | | - File #2 MAIH_PRGRM - 83
 -(L)- - File #2 MAIH_PRGRM - 72
 -(U)- - File #2 MAIH_PRGRM - 84

MECHANICAL PUMP
 1 ISOLATION
 VALVE
 MP11V

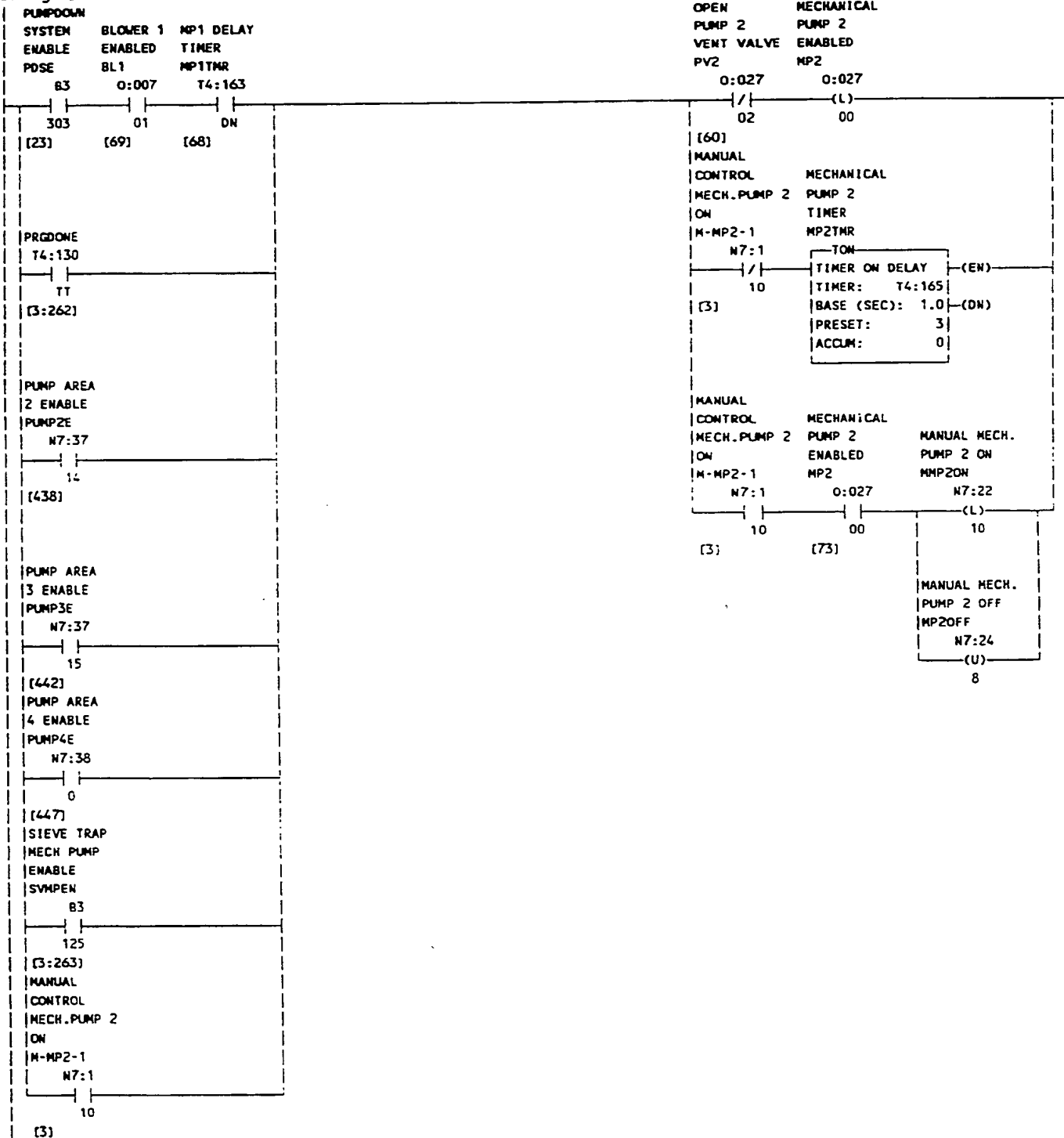
0:010

(L)

03

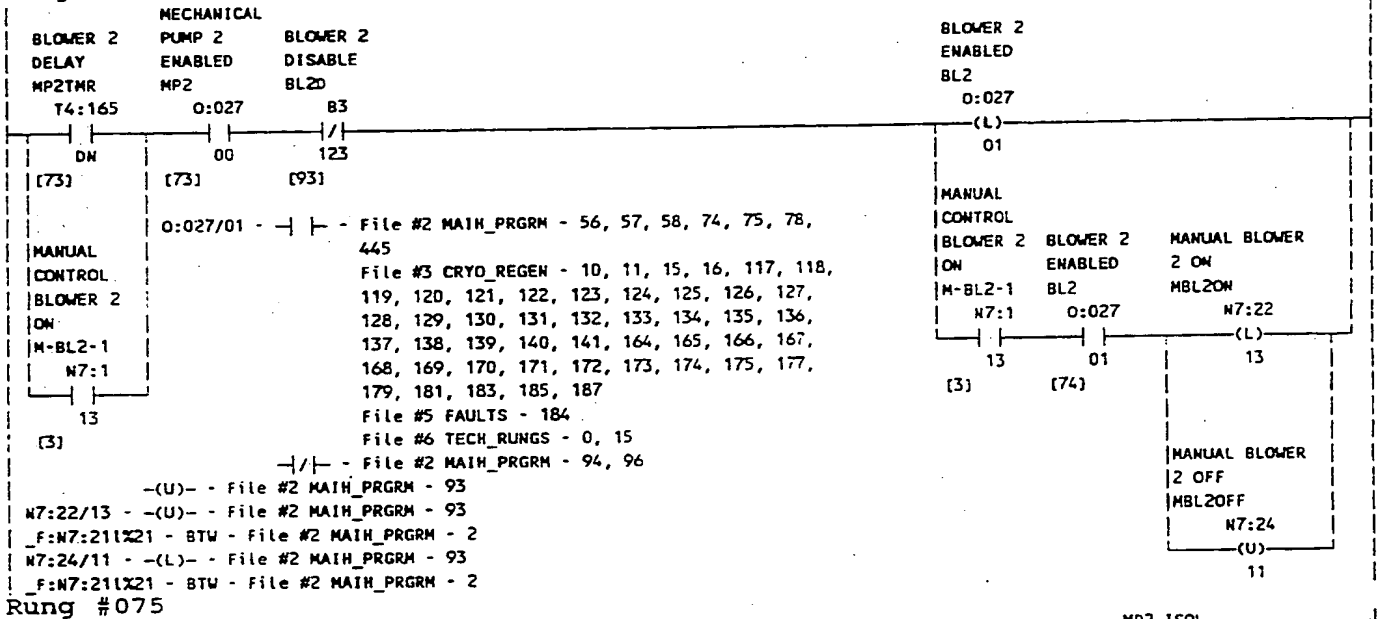
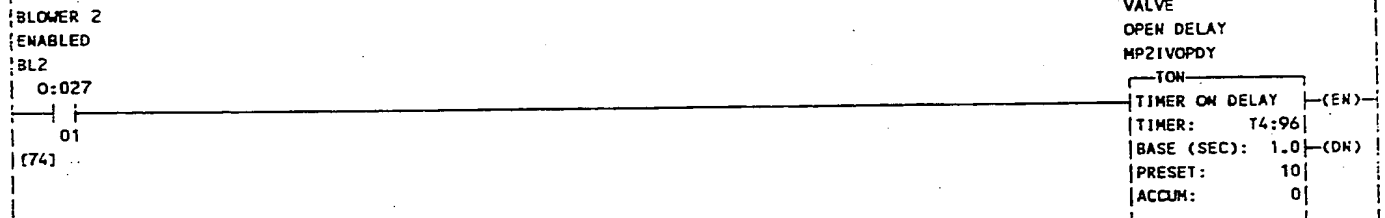
153

Rung #073

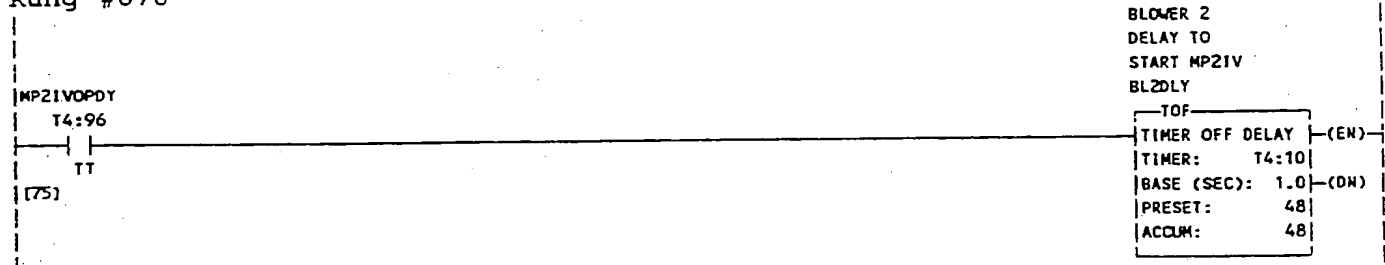


154

0:027/00 - | | - File #2 MAIN_PRGRM - 60,74
 File #5 FAULTS - 184
 File #6 TECH_RUNGS - 0,15
 -(L)- - File #2 MAIN_PRGRM - 73
 -(U)- - File #2 MAIN_PRGRM - 96
 T4:165.DN - | | - File #2 MAIN_PRGRM - 74,78
 N7:22/10 - -(L)- - File #2 MAIN_PRGRM - 73
 -(U)- - File #2 MAIN_PRGRM - 96
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:24/8 - -(L)- - File #2 MAIN_PRGRM - 96
 -(U)- - File #2 MAIN_PRGRM - 73
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
Rung #074

**Rung #075**

T4:96.TT - | | - File #2 MAIN_PRGRM - 76
Rung #076



155

T4:10.TT - | | - File #2 MAIN_PRGRM - 7
| | - File #2 MAIN_PRGRM - 91
Rung #077

| BL2DLY

| T4:10

| TT

| (76)

O:030/03 - | | - File #2 MAIN_PRGRM - 90
-(L)- - File #2 MAIN_PRGRM - 77
-(U)- - File #2 MAIN_PRGRM - 91

MECHANICAL PUMP
2 ISOLATION
VALVE
MP2IV

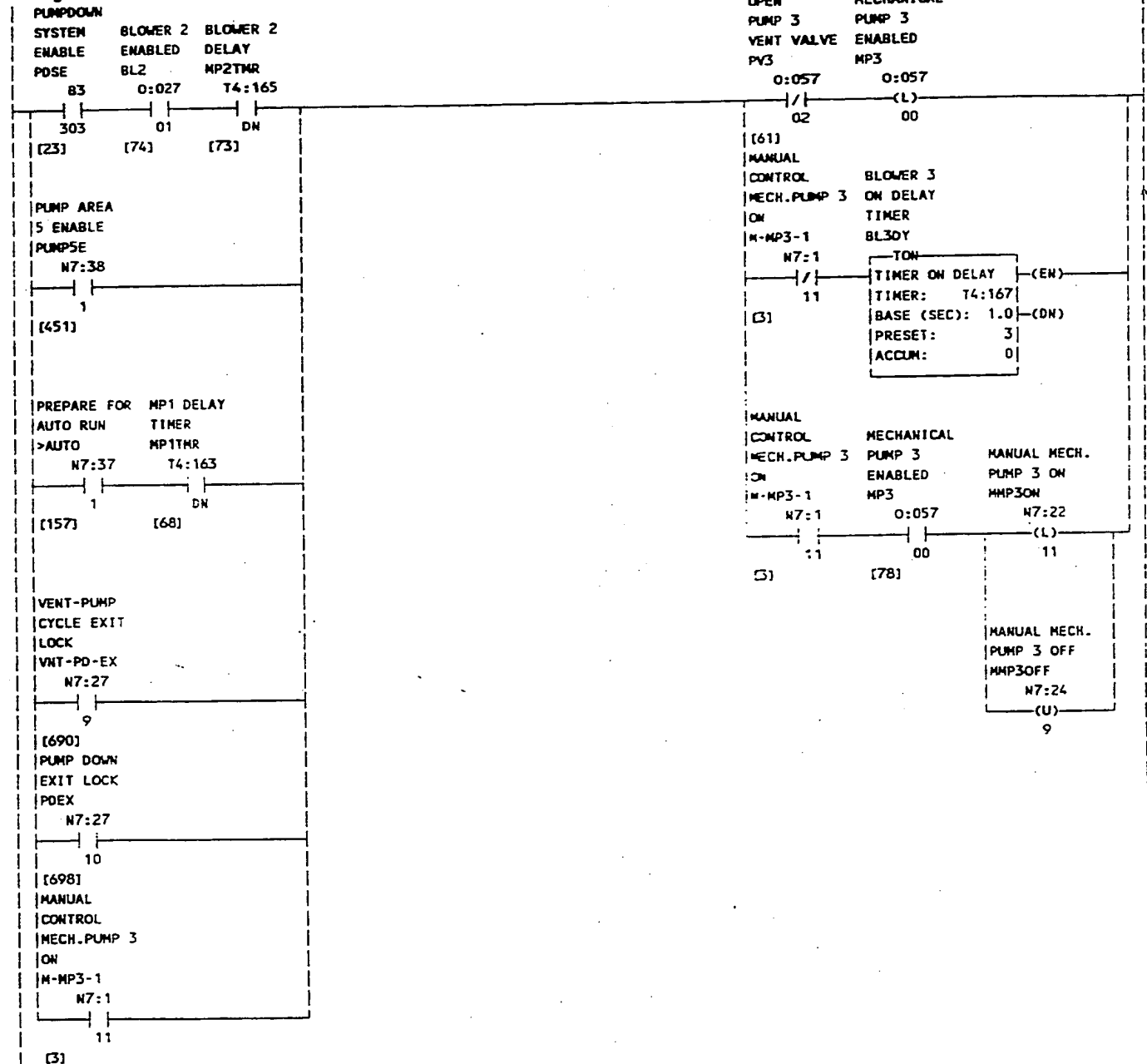
O:030

(L)

03

156

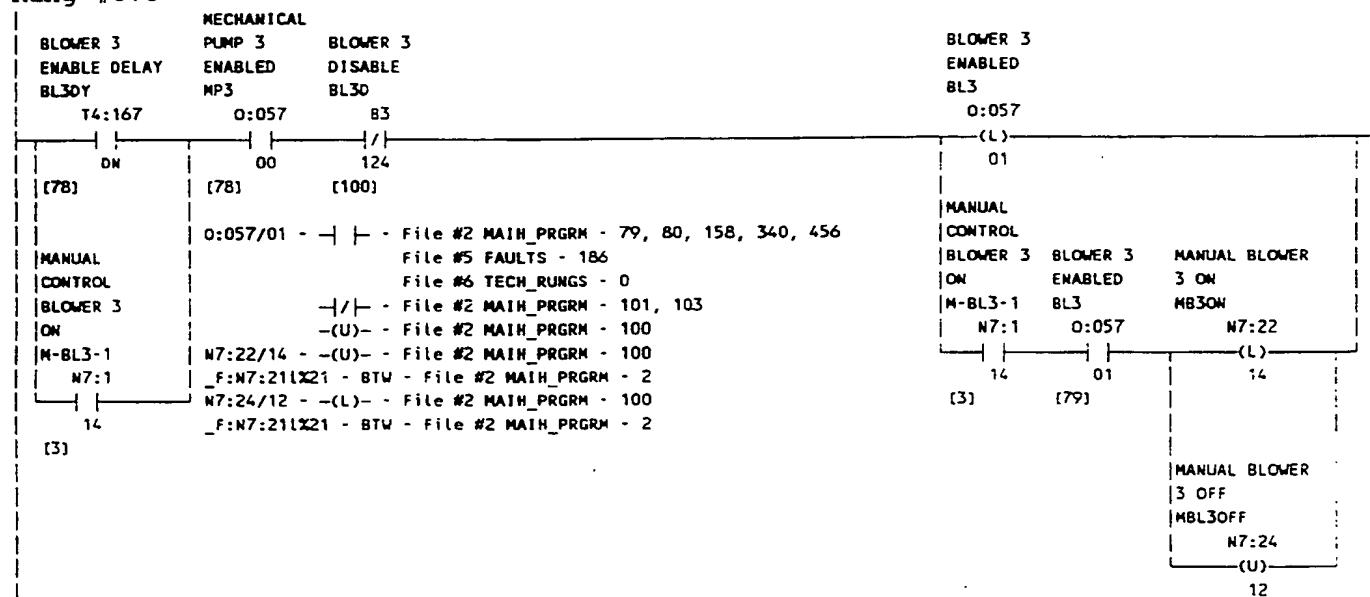
Rung #078



[3] 0:057/00 - | | - File #2 MAIN_PRGRM - 61,79,158
 File #5 FAULTS - 186
 File #6 TECH_RUNGS - 0
 -(L)- - File #2 MAIN_PRGRM - 78
 -(U)- - File #2 MAIN_PRGRM - 103
 T4:167.DN - | | - File #2 MAIN_PRGRM - 79
 N7:22/11 - -(L)- - File #2 MAIN_PRGRM - 78

157

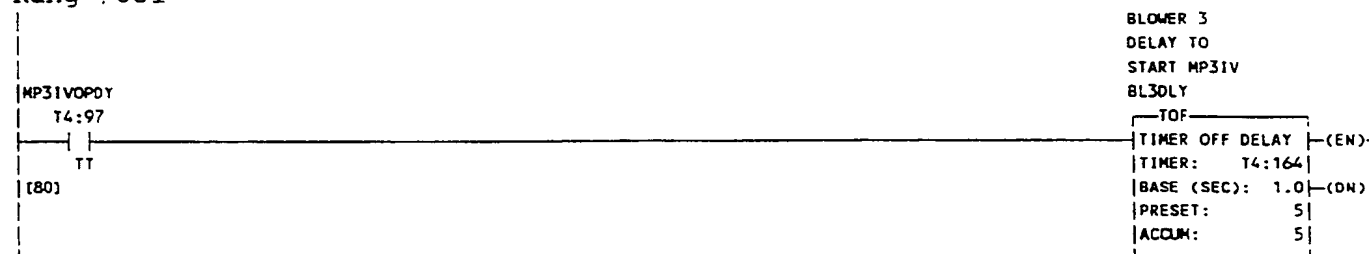
-(U)- - File #2 MAIH_PRGRM - 103
 _F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
 N7:24/9 - -(L)- - File #2 MAIH_PRGRM - 103
 -(U)- - File #2 MAIH_PRGRM - 78
 _F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
 Rung #079



Rung #080

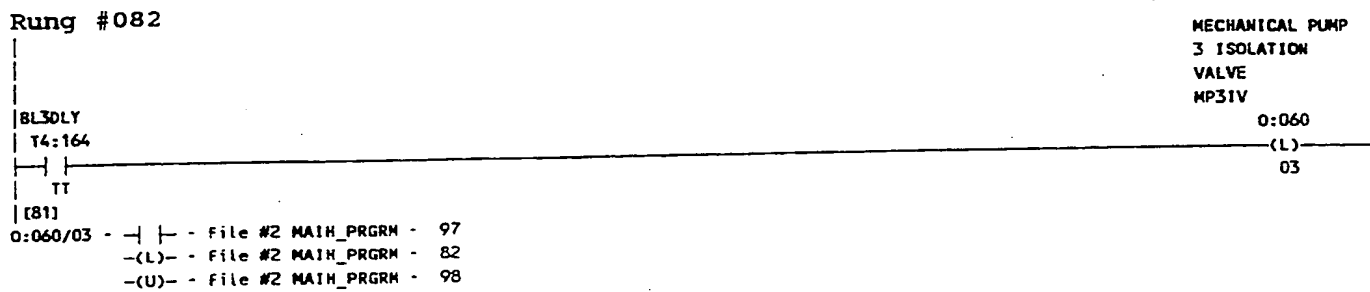


T4:97.TT - | | - File #2 MAIH_PRGRM - 81
 Rung #081

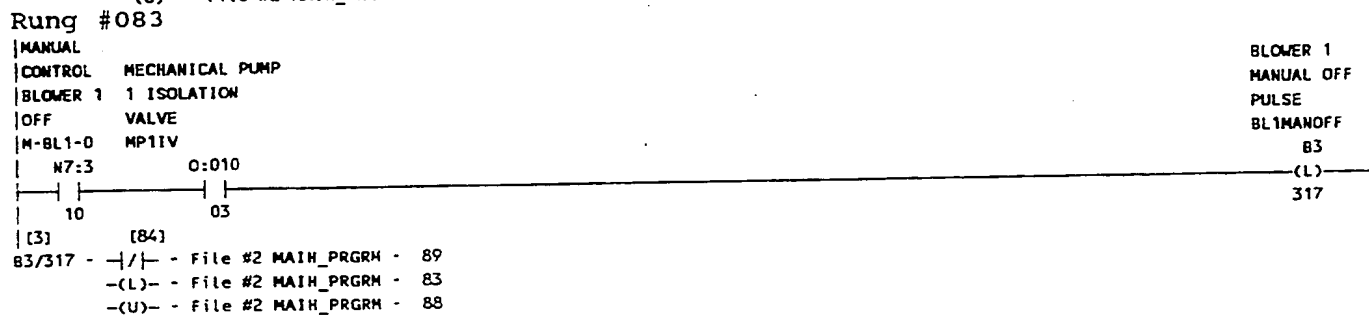


T4:164.TT - | | - File #2 MAIH_PRGRM - 82

Rung #082



Rung #083



160

Rung #086

UNL BL1_PL
T4:289

TT

[85]

0:007/01 - | | - File #2 MAIN_PRGRM - 70, 73, 158, 167, 455
 File #5 FAULTS - 182
 File #6 TECH_RUNGS - 0
 |/| - File #2 MAIN_PRGRM - 87, 89
 -(L)- File #2 MAIN_PRGRM - 69
 83/122 - |/| - File #2 MAIN_PRGRM - 69
 N7:22/12 - -(L)- File #2 MAIN_PRGRM - 69
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:24/10 - -(U)- File #2 MAIN_PRGRM - 69
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

 BLOWER 1
 ENABLED
 BL1
 0:007

(U)

01

 BLOWER 1
 DISABLE
 BL1D

83

()

122

 MANUAL BLOWER
 1 ON
 MBL1ON

N7:22

(U)

12

 MANUAL BLOWER
 1 OFF
 MBL1OFF

N7:24

(L)

10

Rung #087

 BLOWER 1
 ENABLED
 BL1

0:007

|/|

01

[86]

 BLOWER 1
 OFF-AUTO
 PULSE
 BL1OFFPLSE

TON

TIMER ON DELAY

(EN)

TIMER: T4:292

BASE (SEC): 1.0 (DN)

PRESET: 8

ACCUM: 0

 T4:292.DN - | | - File #2 MAIN_PRGRM - 88
 T4:292.TT - | | - File #2 MAIN_PRGRM - 89

Rung #088

 BL1OFFPLSE
 T4:292

DN

[87]

83/317 - |/| - File #2 MAIN_PRGRM - 89
 -(L)- File #2 MAIN_PRGRM - 83
 -(U)- File #2 MAIN_PRGRM - 88

 BLOWER 1
 MANUAL OFF
 PULSE
 BL1MANOFF

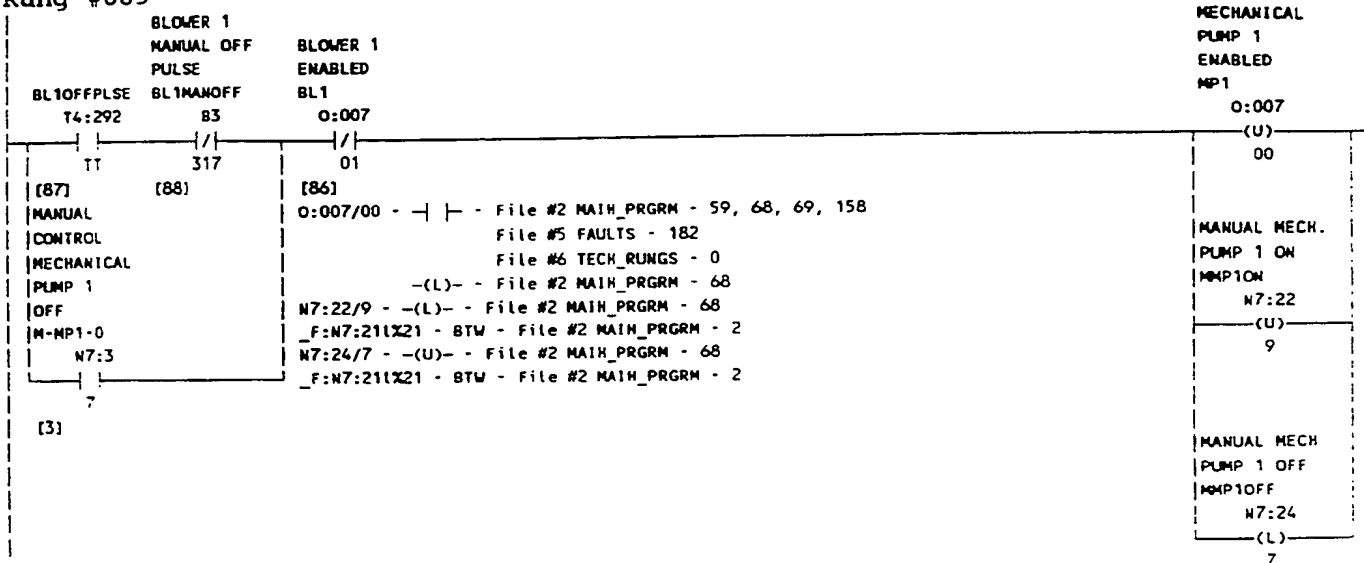
83

(U)

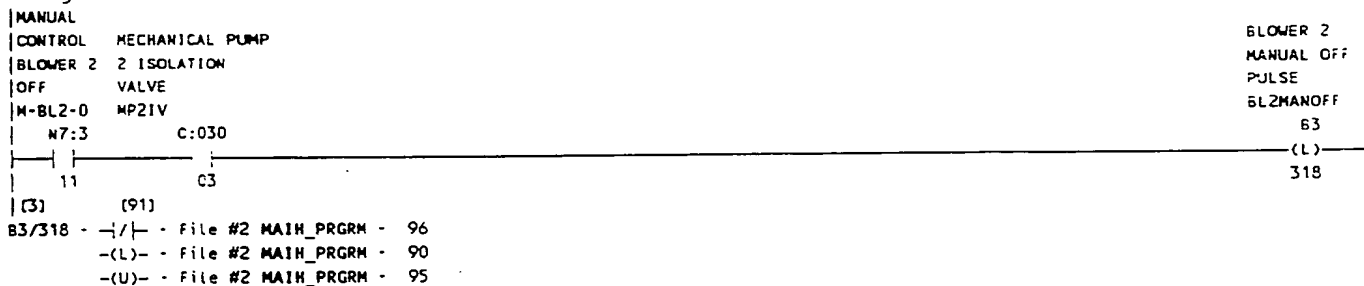
317

161

Rung #089

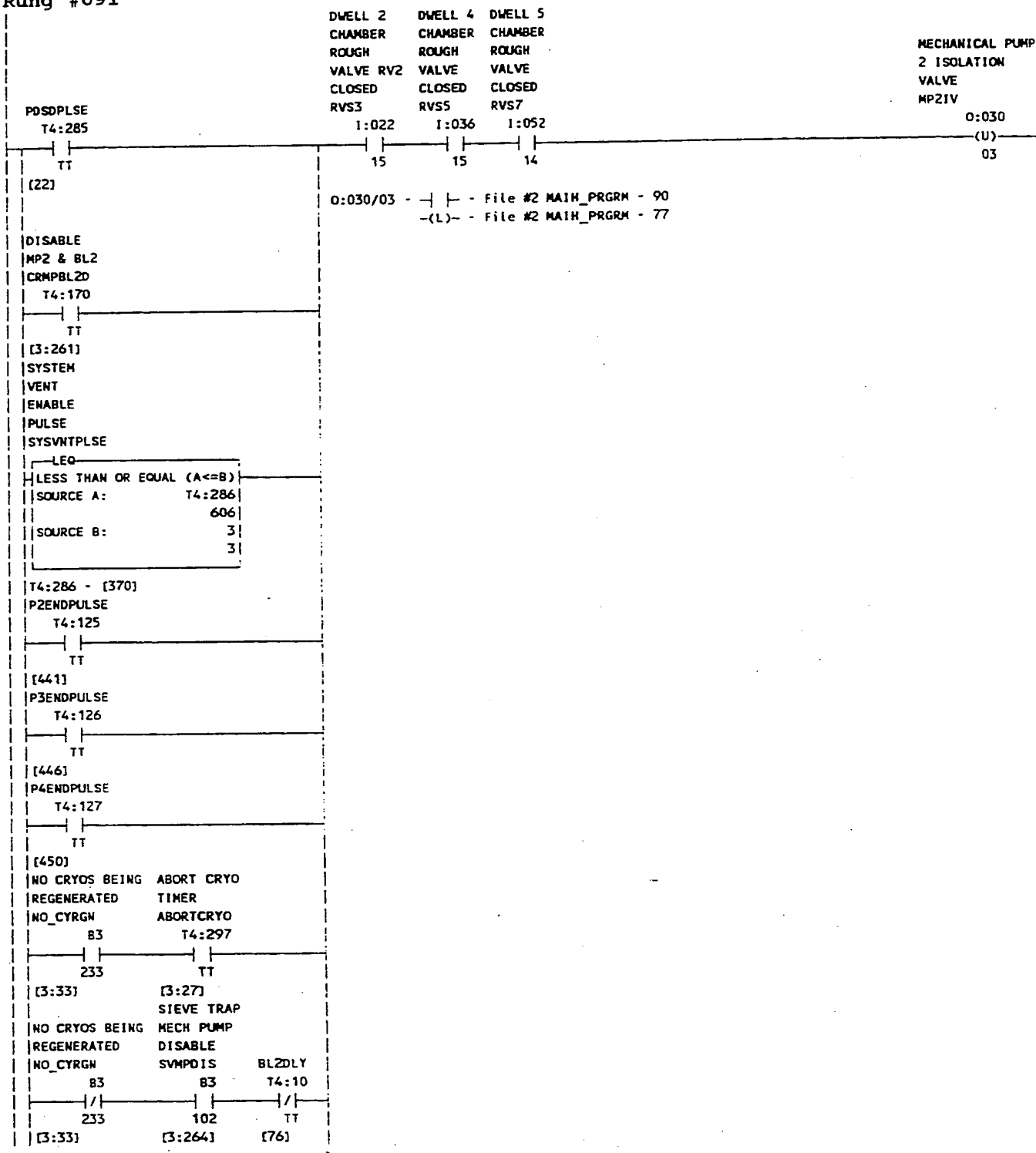


Rung #090

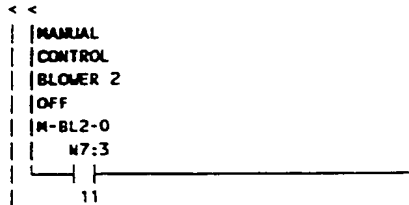


162

Rung #091

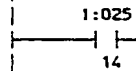


163



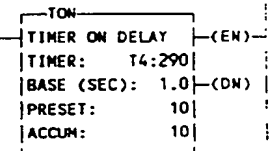
(3)
Rung #092

MECHANICAL PUMP
2 ISOLATION
VALVE CLOSE
SENSOR
MP21VCL



T4:290.TT - | | - File #2 MAIN_PRGRM - 93

UNLATCH BL2
PULSE
UNL_BL2_PL

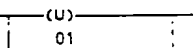


Rung #093

UNL_BL2_PL
T4:290



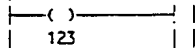
BLOWER 2
ENABLED
BL2
O:027



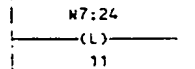
(92)

O:027/01 - | | - File #2 MAIN_PRGRM - 56, 57, 58, 74, 75, 78, 445
 File #3 CRYO_REGEN - 10, 11, 15, 16, 117, 118, 119, 120, 121, 122, 123, 124,
 125, 126, 127, 128, 129, 130, 131, 132, 133, 134, 135, 136, 137, 138, 139,
 140, 141, 164, 165, 166, 167, 168, 169, 170, 171, 172, 173, 174, 175, 177,
 179, 181, 183, 185, 187
 File #5 FAULTS - 184
 File #6 TECH_RUNGS - 0, 15
 -|/| - File #2 MAIN_PRGRM - 94, 96
 -(L)- - File #2 MAIN_PRGRM - 74
 B3/123 - |/| - File #2 MAIN_PRGRM - 74
 M7:24/11 - -(U)- - File #2 MAIN_PRGRM - 74
 _F:M7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
 M7:22/13 - -(L)- - File #2 MAIN_PRGRM - 74
 _F:M7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

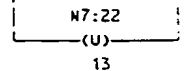
BLOWER 2
DISABLE
BL2D



MANUAL BLOWER
2 OFF
MBL2OFF



MANUAL BLOWER
2 ON
MBL2ON



164

Rung #094

BLOWER 2
ENABLED
BL2

0:027

01

[93]

BLOWER 2
OFF-AUTO
PULSE
BL2OFFPLSE

TON	
TIMER ON DELAY	(EN)
TIMER: T4:293	
BASE (SEC): 1.0	(DN)
PRESET: 5	
ACCUM: 5	

T4:293.DN - | | - File #2 MAIN_PRGRM - 95
T4:293.TT - | | - File #2 MAIN_PRGRM - 96

Rung #095

BL2OFFPLSE
T4:293

DN

[94]

83/318 - | | - File #2 MAIN_PRGRM - 96
-(L)- - File #2 MAIN_PRGRM - 90
-(U)- - File #2 MAIN_PRGRM - 95

BLOWER 2
MANUAL OFF
PULSE
BL2MANOFF

B3

(U)

318

Rung #096

BLOWER 2
MANUAL OFF
PULSE
BL2OFFPLSE
T4:293

B3
318

BLOWER 2
ENABLED
BL2
0:027

TT

[95]

[93]

0:027/00 - | | - File #2 MAIN_PRGRM - 60, 73, 74
File #5 FAULTS - 184
File #6 TECH_RUNGS - 0, 15
-(L)- - File #2 MAIN_PRGRM - 73
N7:22/10 - -(L)- - File #2 MAIN_PRGRM - 73
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:24/8 - -(U)- - File #2 MAIN_PRGRM - 73
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

8

(3)

MECHANICAL
PUMP 2
ENABLED
MP2

0:027

(U)

00

MANUAL MECH.
PUMP 2 ON
MMP2ON

N7:22

(U)

10

MANUAL MECH.
PUMP 2 OFF
MP2OFF

N7:24

(L)

8

Rung #097

MANUAL
CONTROL MECHANICAL PUMP
BLOWER 3 3 ISOLATION
OFF VALVE
M-BL3-0 MP3IV
N7:3 0:060

12

03

[3]

[98]

83/319 - | | - File #2 MAIN_PRGRM - 103

BLOWER 3
MANUAL OFF
PULSE
BL3MANOFF

B3

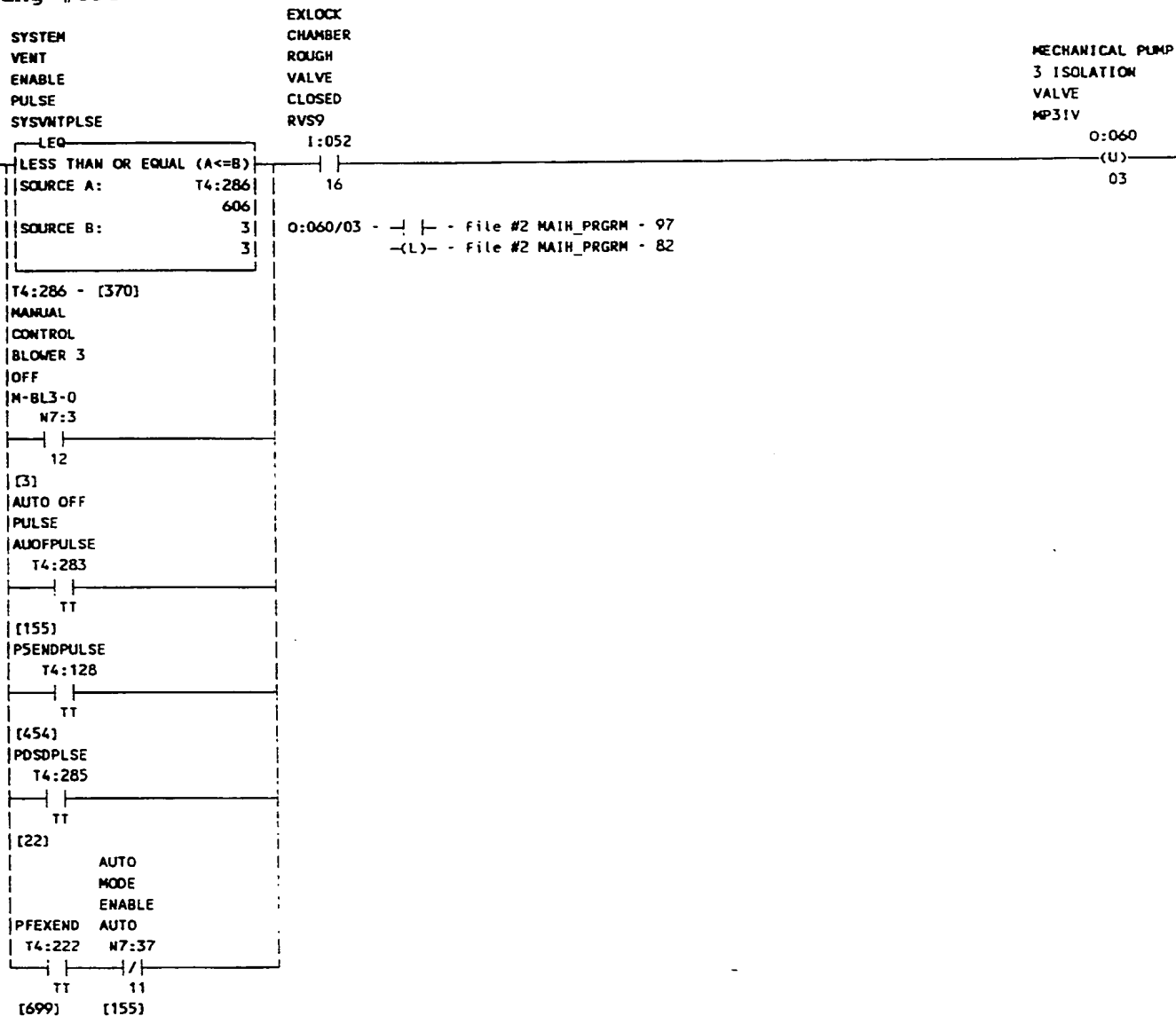
(L)

319

165

-(L)- - File #2 MAIN_PRGRM -
 -(U)- - File #2 MAIN_PRGRM - 102

Rung #098



Rung #099



166

Rung #100

UNL_BL3_PL
T4:291

TT

[99]

O:057/01 - | | - File #2 MAIH_PRGRM - 79, 80, 158, 340, 456

File #5 FAULTS - 186

File #6 TECH_RUNGS - 0

-|/| - File #2 MAIH_PRGRM - 101, 103

-(L)- - File #2 MAIH_PRGRM - 79

83/124 - |/| - File #2 MAIH_PRGRM - 79

N7:22/14 - -(L)- - File #2 MAIH_PRGRM - 79

_F:N7:21LX21 - BTW - File #2 MAIH_PRGRM - 2

N7:24/12 - -(U)- - File #2 MAIH_PRGRM - 79

_F:N7:21LX21 - BTW - File #2 MAIH_PRGRM - 2

BLOWER 3
ENABLED
BL3

O:057

(U)

01

BLOWER 3
DISABLE
BL3D

83

()

124

MANUAL BLOWER
3 ON
MB3ON

N7:22

(U)

14

MANUAL BLOWER
3 OFF
MBL3OFF

N7:24

(L)

12

Rung #101

BLOWER 3

ENABLED

BL3

O:057

01

[100]

BLOWER 3
OFF-AUTO
PULSE
BL3OFFPLSE

TON

TIMER ON DELAY (EN)

TIMER: T4:294

BASE (SEC): 1.0 (DN)

PRESET: 5

ACCU: 0

T4:294.DN - | | - File #2 MAIH_PRGRM - 102

T4:294.TT - | | - File #2 MAIH_PRGRM - 103

Rung #102

BL3OFFPLSE

T4:294

DN

[101]

B3/319 - |/| - File #2 MAIH_PRGRM - 103

-(L)- - File #2 MAIH_PRGRM - 97

-(U)- - File #2 MAIH_PRGRM - 102

BLOWER 3
MANUAL OFF
PULSE
BL3MANOFF

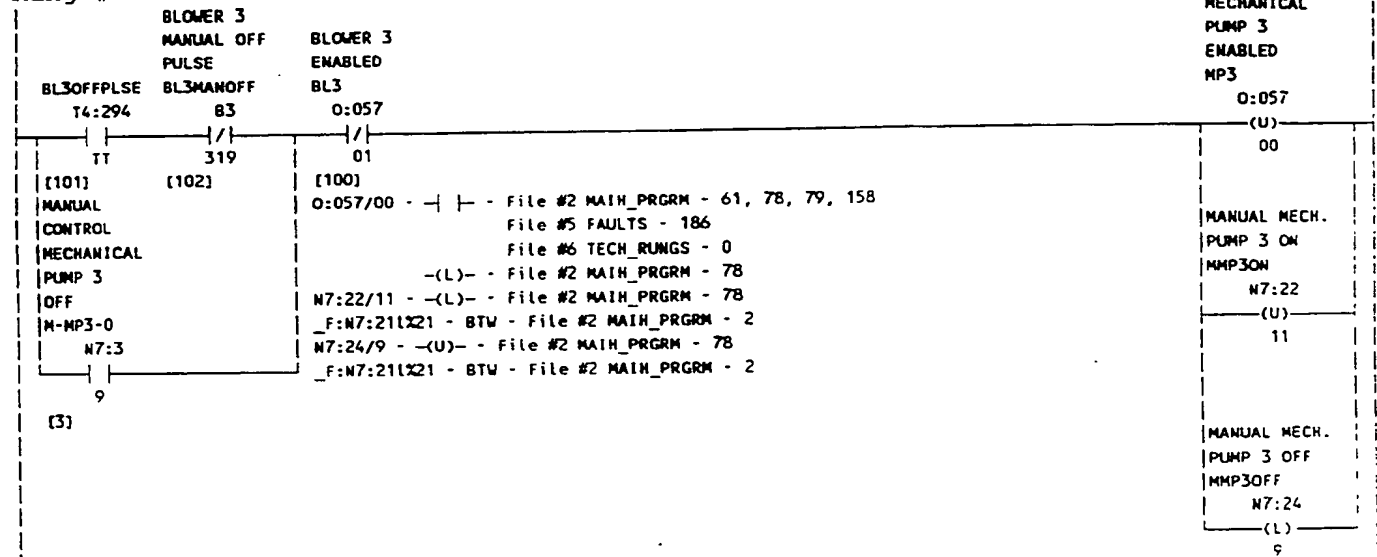
83

(U)

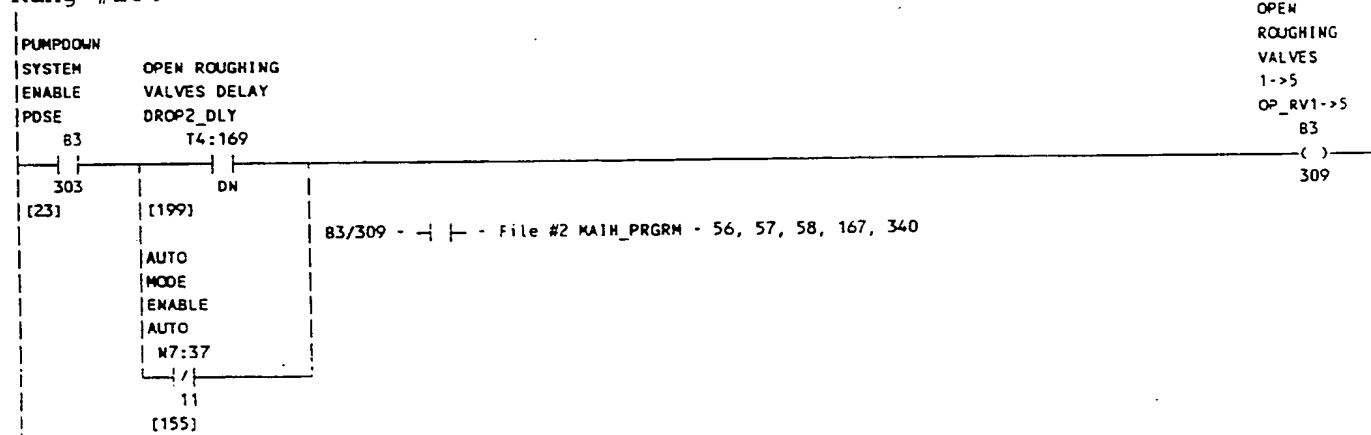
319

167

Rung #103

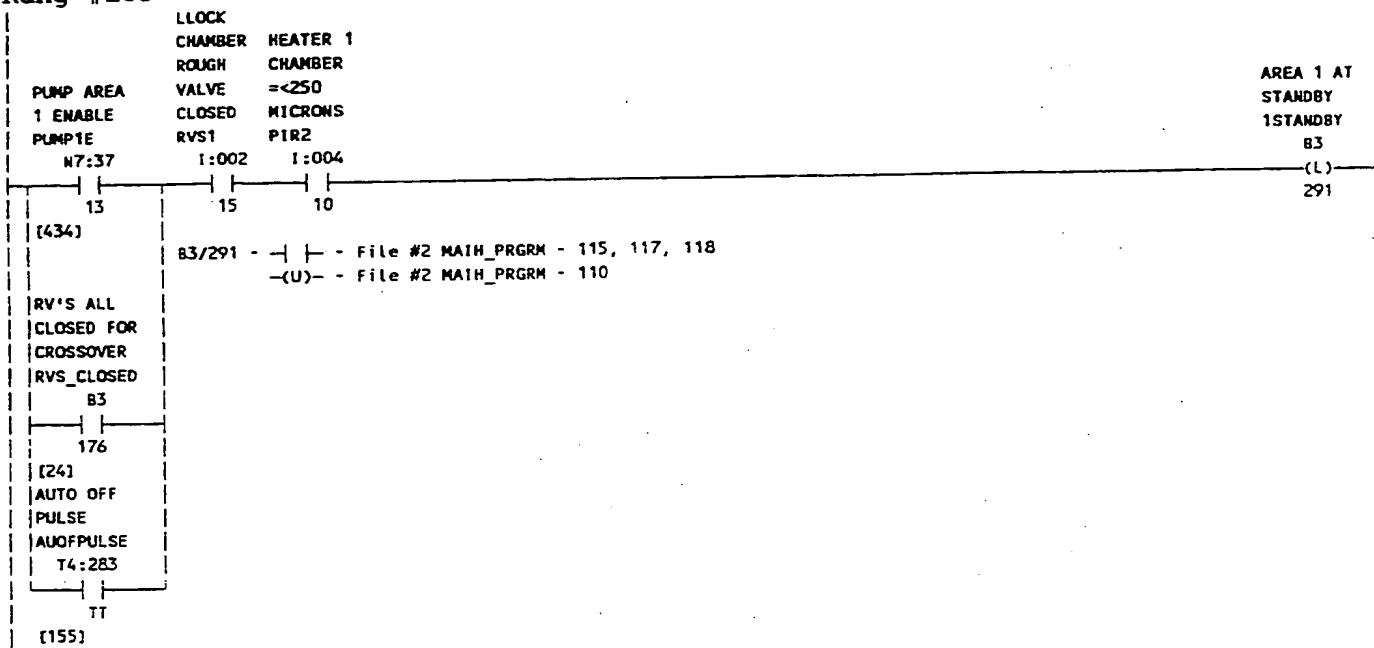


Rung #104

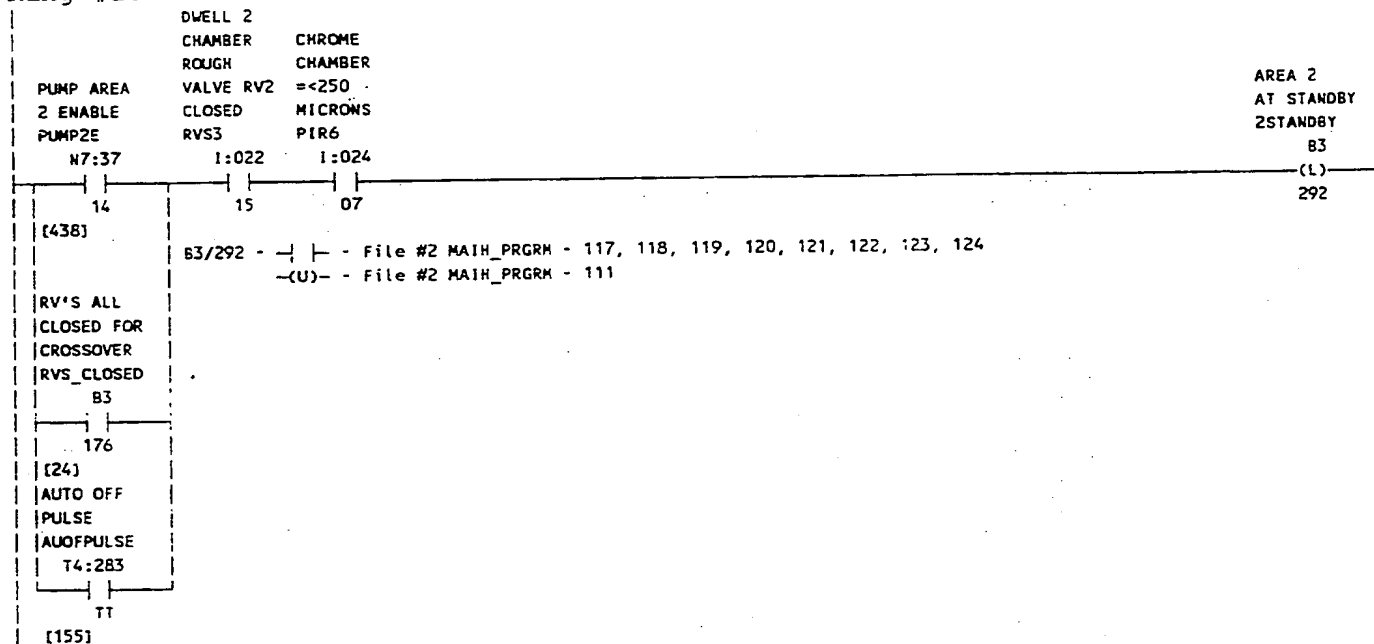


168

Rung #105

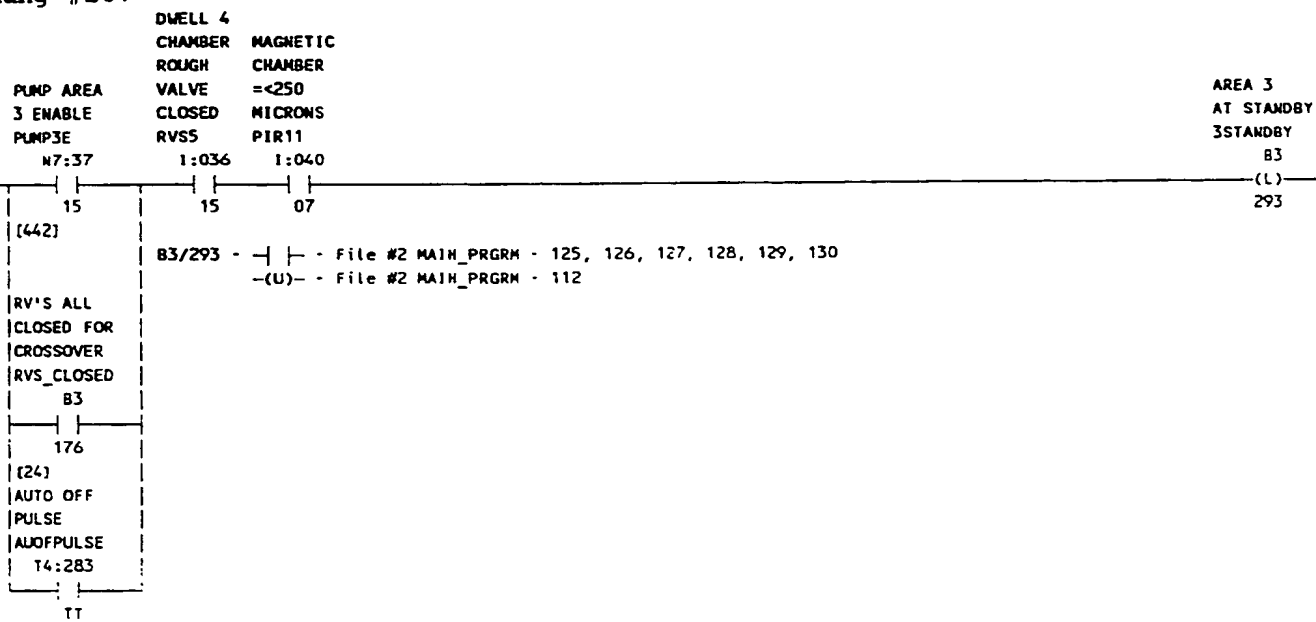


Rung #106

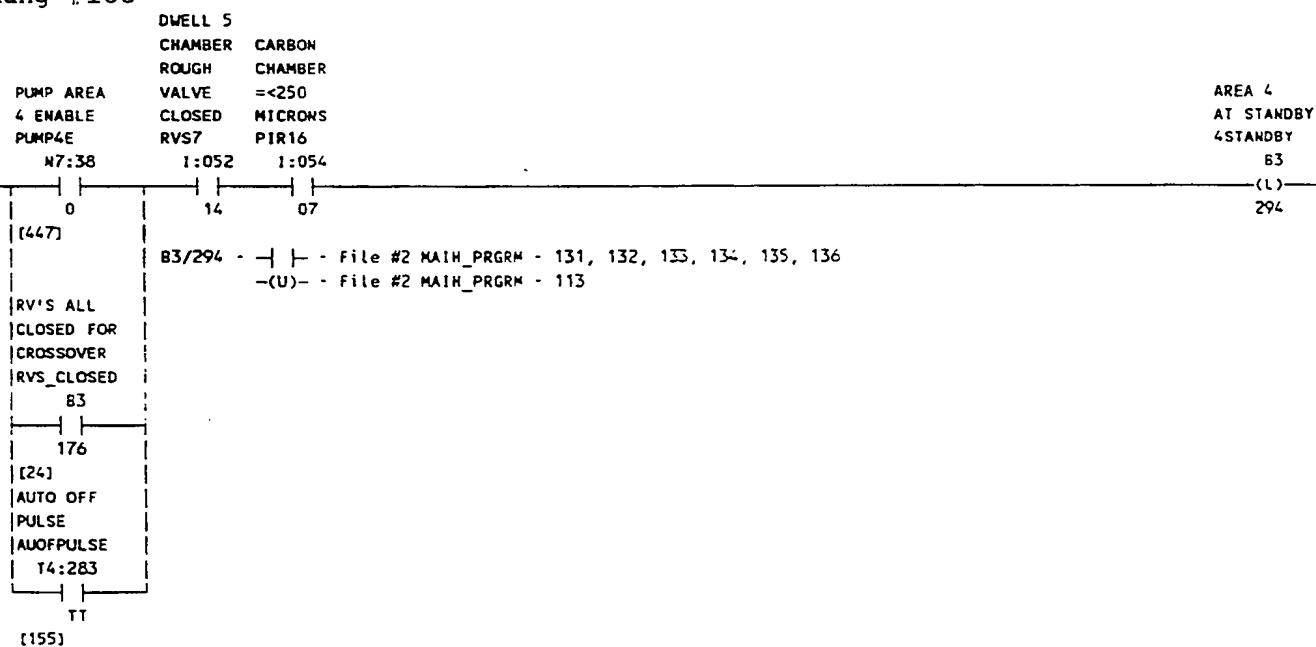


169

Rung #107

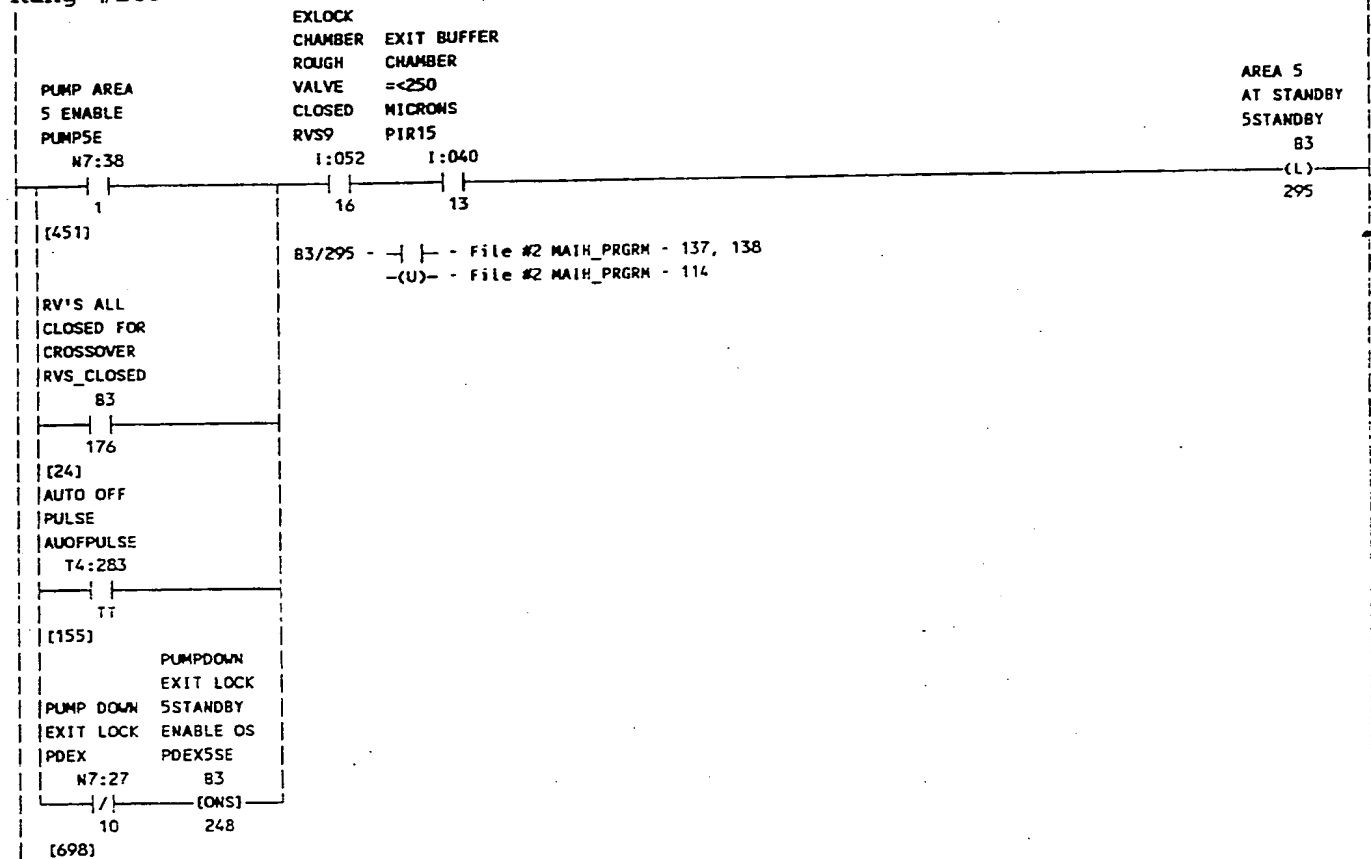


Rung #108



170

Rung #109



191

Rung #110

SYSTEM
VENT
ENABLE
SYSVME
N7:37

AREA 1 AT
STANDBY
1STANDBY
83

5

[368]

B3/291 - | | - File #2 MAIN_PRGRM - 115, 117, 118
-(L)- - File #2 MAIN_PRGRM - 105

VENT AREA
1 ENABLE
VENT1E
N7:37

6

[405]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[157]

reset
RESET
N7:17

15

[3]

COMPRESSOR
2 REGEN-
ERATION
PROGRAM
CYRGN2

83

322

[3:34]

(U)
291

172

Rung #111

SYSTEM
VENT
ENABLE
SYSVTE
N7:37

AREA 2
AT STANDBY
2STANDBY
B3
(U)
292

5
[368]

B3/292 - | | - File #2 MAIH_PRGRM - 117, 118, 119, 120, 121, 122, 123, 124
-(L)- - File #2 MAIH_PRGRM - 106

VENT AREA
2 ENABLE
VENT2E
N7:37

7

[411]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[157]

reset

RESET

N7:17

15

[3]

COMPRESSOR

3 REGEN-

ERATION

PROGRAM

CYRGN3

B3

323

[3:38]

COMPRESSOR

4 REGEN-

ERATION

PROGRAM

CYRGN4

B3

324

[3:42]

COMPRESSOR

5 REGEN-

ERATION

PROGRAM

CYRGN5

B3

325

[3:46]

173

Rung #112

SYSTEM
VENT
ENABLE
SYSWTE
W7:37

AREA 3
AT STANDBY
3STANDBY
83

(U)
293

5
(368)

83/293 - | | - File #2 MAIN_PRGRM - 125, 126, 127, 128, 129, 130
-(L)- - File #2 MAIN_PRGRM - 107

VENT AREA
3 ENABLE
VENT3E
W7:37

8
(418)

PREPARE FOR
AUTO RUN
>AUTO
W7:37

1
(157)

reset
RESET
W7:17

15
(3)

COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGN5
83

325
(3:46)

COMPRESSOR
6 REGEN-
ERATION
PROGRAM
CYRGN6
83

326
(3:52)

174

Rung #113

SYSTEM
VENT
ENABLE
SYSV:TE
N7:37

AREA 4
AT STANDBY
4STANDBY

83

(U)

294

5

[368]

83/294 - | | - File #2 MAIN_PRGRM - 131, 132, 133, 134, 135, 136
-(L)- - File #2 MAIN_PRGRM - 108

VENT AREA
4 ENABLE
VENT4E
N7:37

9

[425]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[157]

reset

RESET

N7:17

15

[3]

COMPRESSOR

7 REGEN-

ERATION

PROGRAM

CYRGN7

83

327

[3:57]

COMPRESSOR

8 REGEN-

ERATION

PROGRAM

CYRGN8

83

328

[3:63]

175

Rung #114

SYSTEM
VENT
ENABLE
SYSVNT
N7:37

AREA 5
AT STANDBY
SSSTANDBY
83
(U)
295

5
[368]

83/295 - | | - File #2 MAIN_PRGRM - 137, 138
-(L)- - File #2 MAIN_PRGRM - 109

VENT AREA
S ENABLE
VENTSE
N7:37

10

[430]

PREPARE FOR
AUTO RUN
>AUTO

N7:37
1

[157]

reset

RESET

N7:17

15

[3]

COMPRESSOR

7 REGEN-

ERATION

PROGRAM

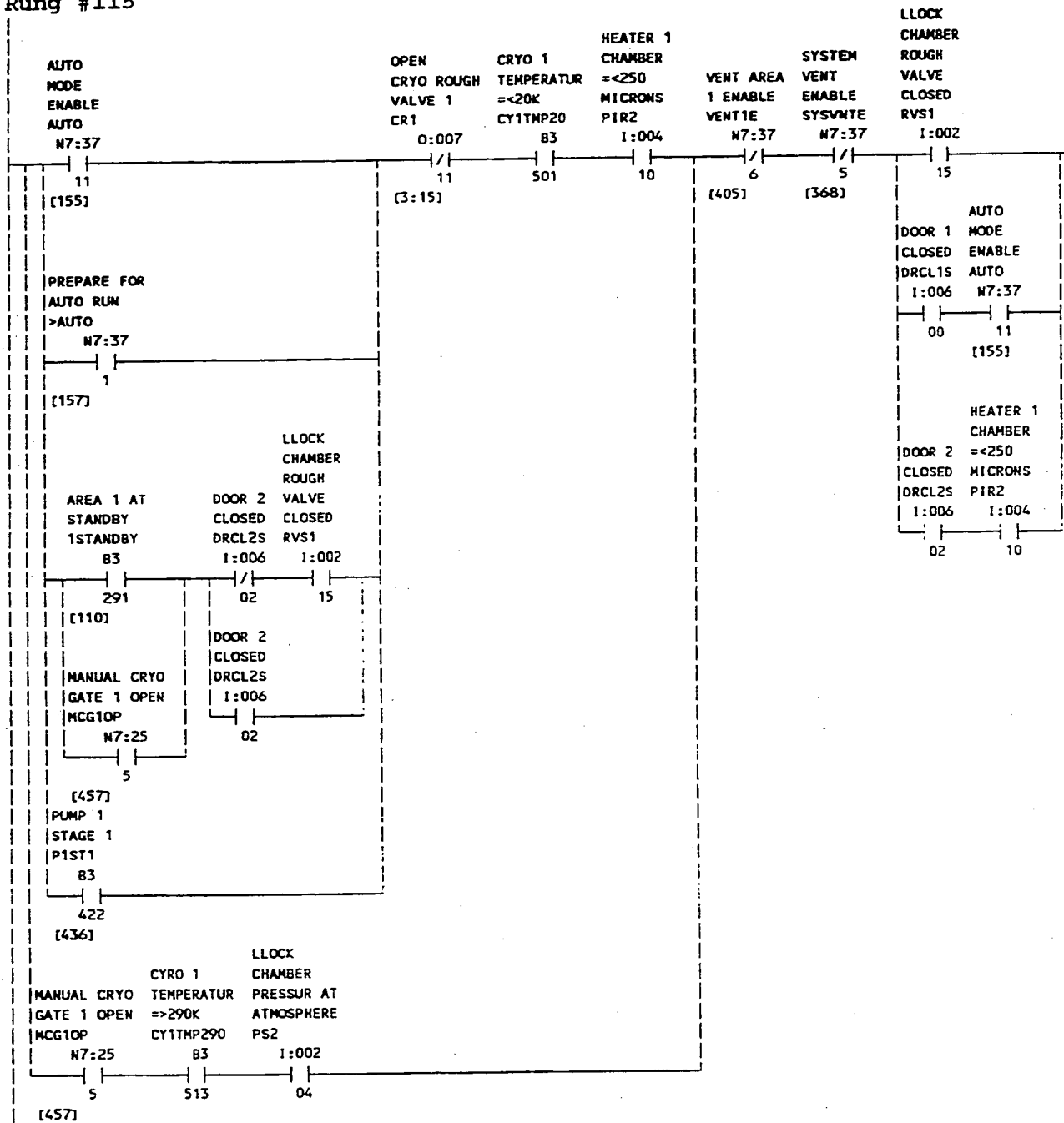
CYRGM7

83

327

[3:57]

Rung #115



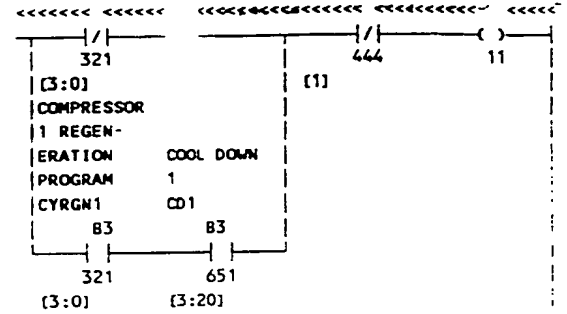
COMPRESSOR

```

1 REGEN-          FIRST SCAN    CRYO GATE
ERATION          AFTER POWER    HEATER 1
PROGRAM          LOSS           CHAMBER
CYRGN1          PWR_ON_DLY      HV1
83              83              0:011

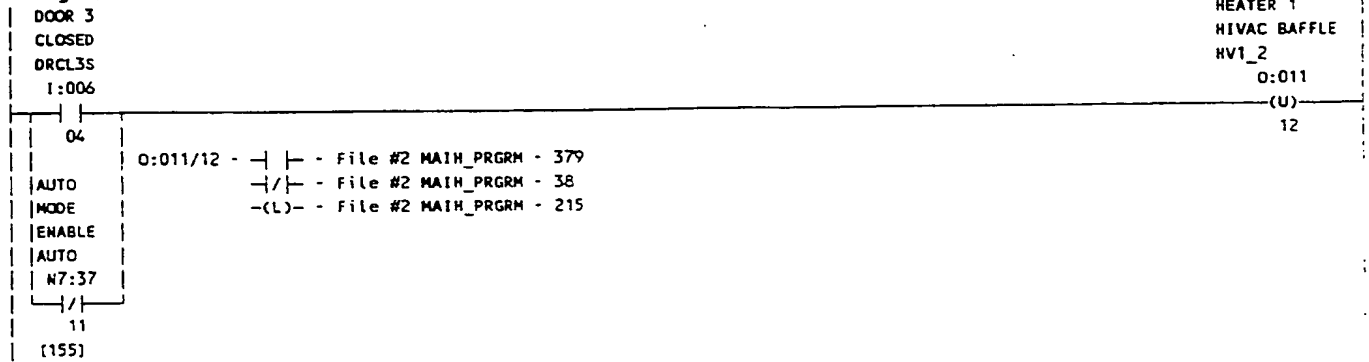
```


197



0:011/11 - | | - File #5 FAULTS - 69
 File #6 TECH_RUNGS - 6
 | | - File #5 FAULTS - 117
 - () - File #2 MAIN_PRGRM - 115

Rung #116

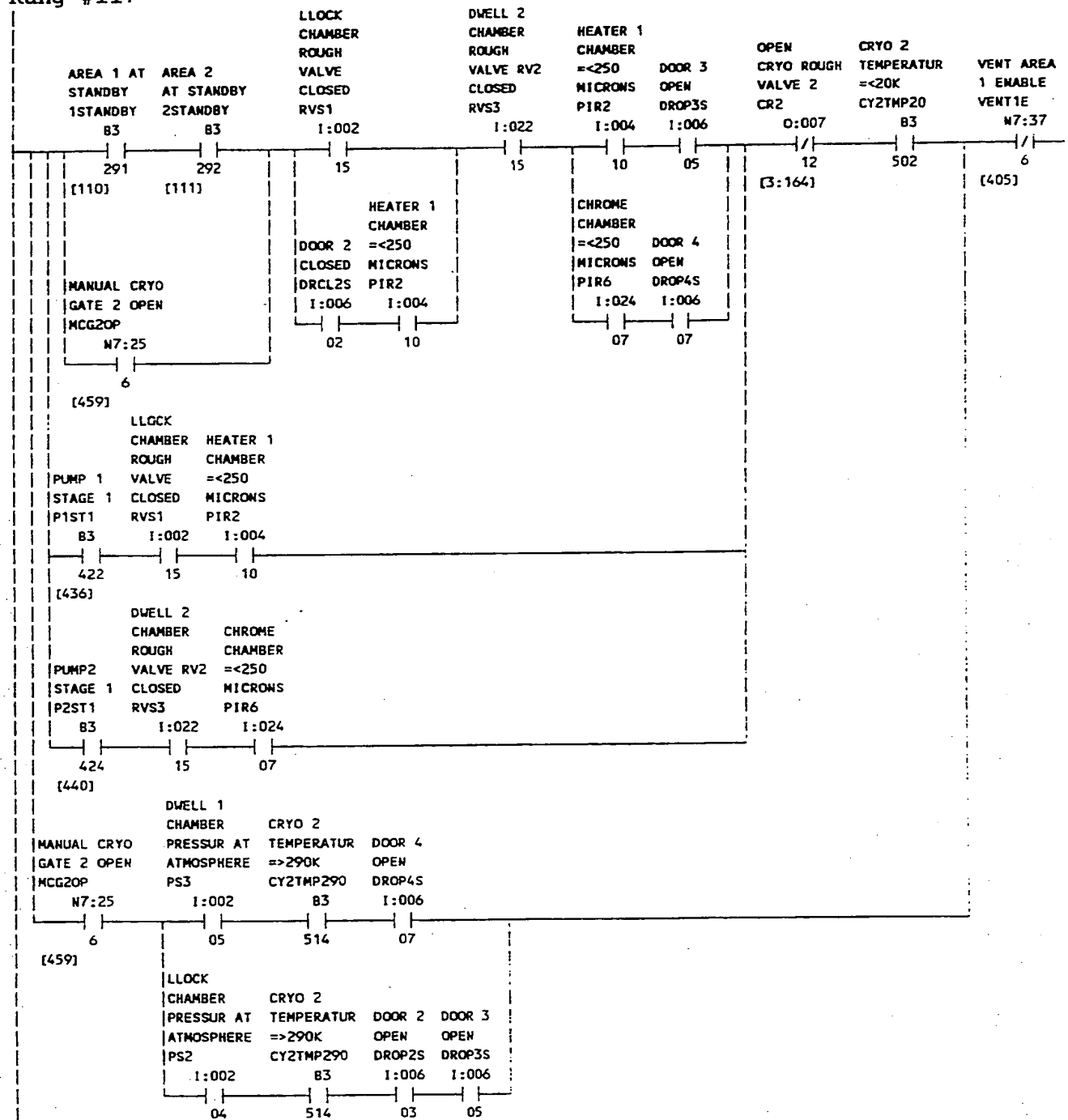


0:011/12 - | | - File #2 MAIN_PRGRM - 379
 | | - File #2 MAIN_PRGRM - 38
 - (L) - File #2 MAIN_PRGRM - 215

HEATER 1
 H1VAC BAFFLE
 HV1_2
 0:011
 (U)
 12

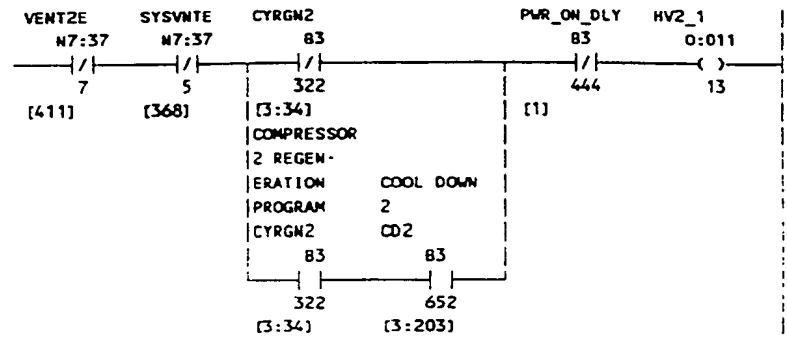
198

Rung #117



VENT AREA 2 ENABLE	SYSTEM VENT ENABLE	COMPRESSOR 2 REGENERATION PROGRAM	FIRST SCAN AFTER POWER LOSS	CRYO GATE SOLENOID 1 HEATER 2 CHAMBER
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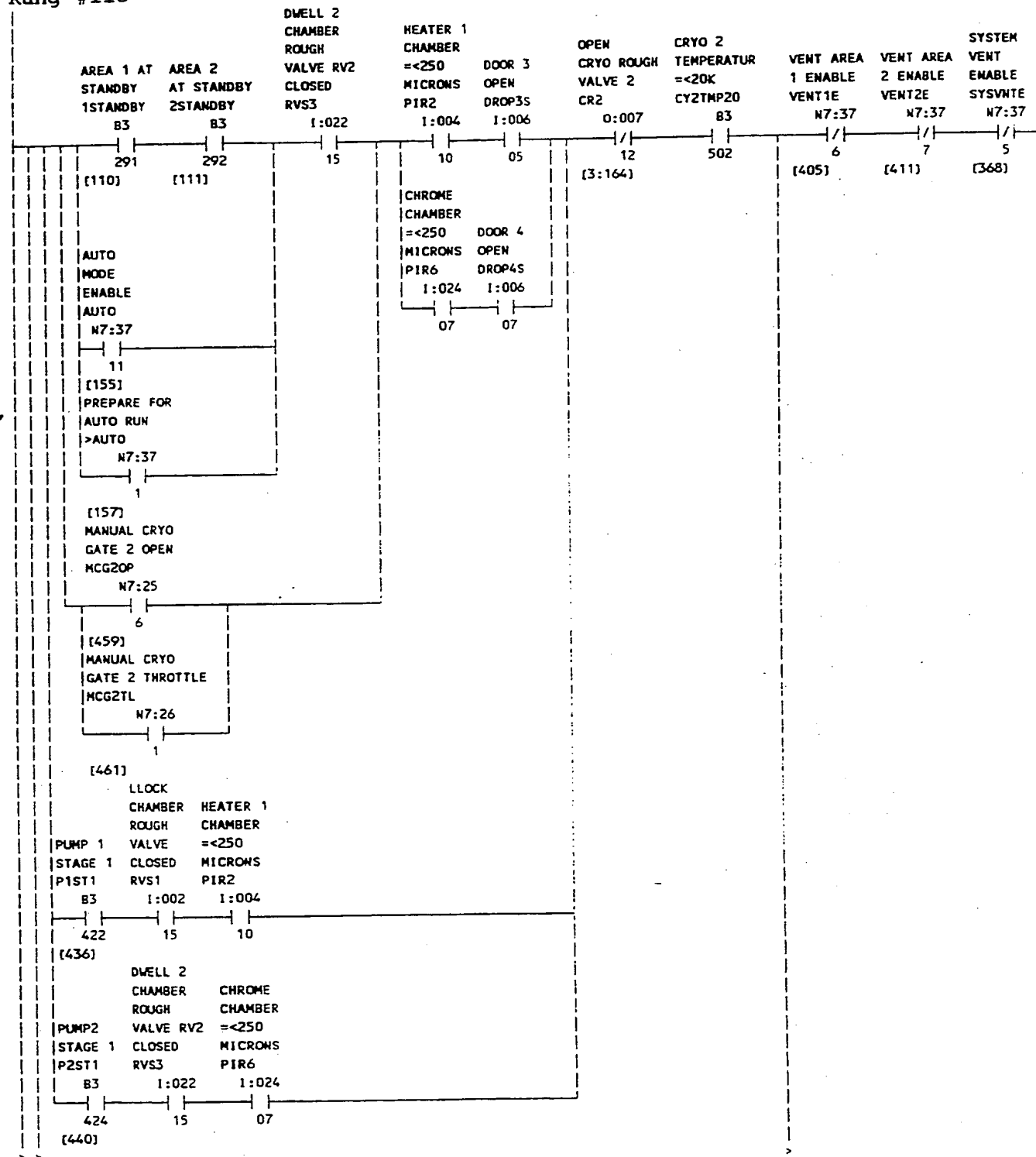
179



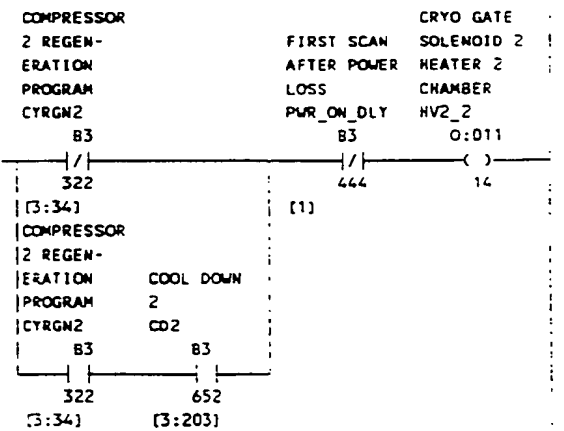
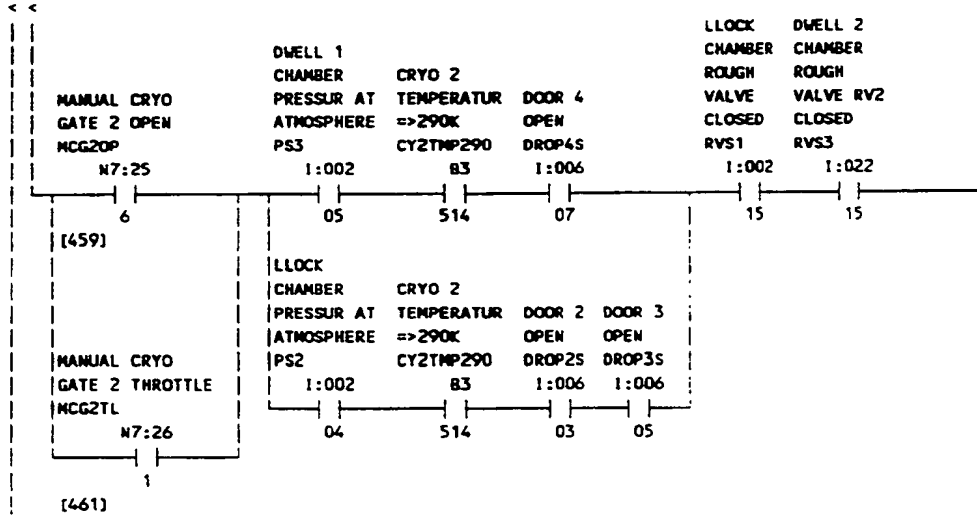
O:011/13 - | | - File #5 FAULTS - 71
 File #6 TECH_RUNGS - 6
 -|/| - File #5 FAULTS - 94,119
 -() - File #2 MAIN_PRGRM - 117

180

Rung #118



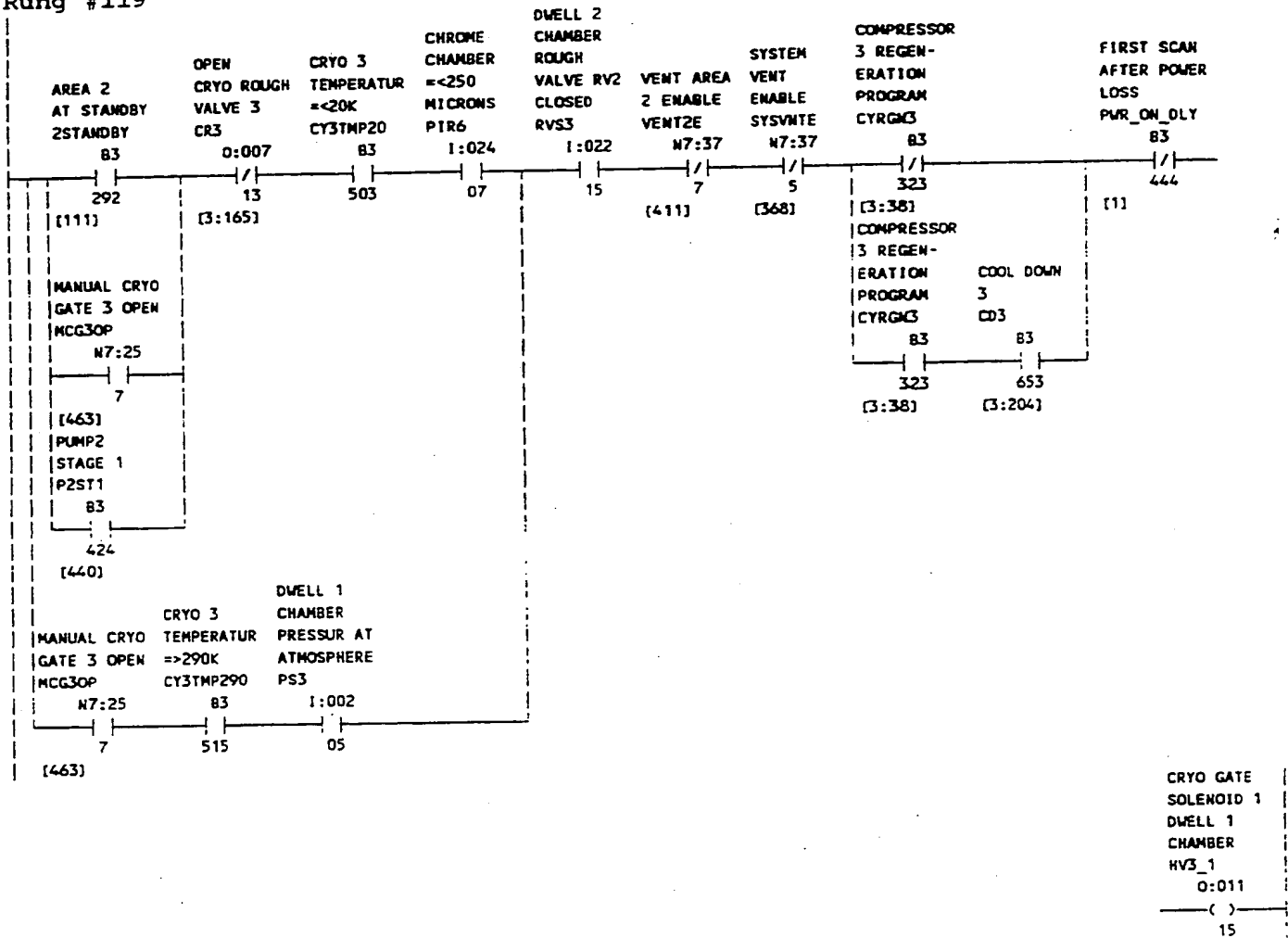
181



0:011/14 - | | - File #5 FAULTS - 71,94
 File #6 TECH_RUNGS - 6
 -|/| - File #5 FAULTS - 119
 -() - File #2 MAIN_PRGRM - 118

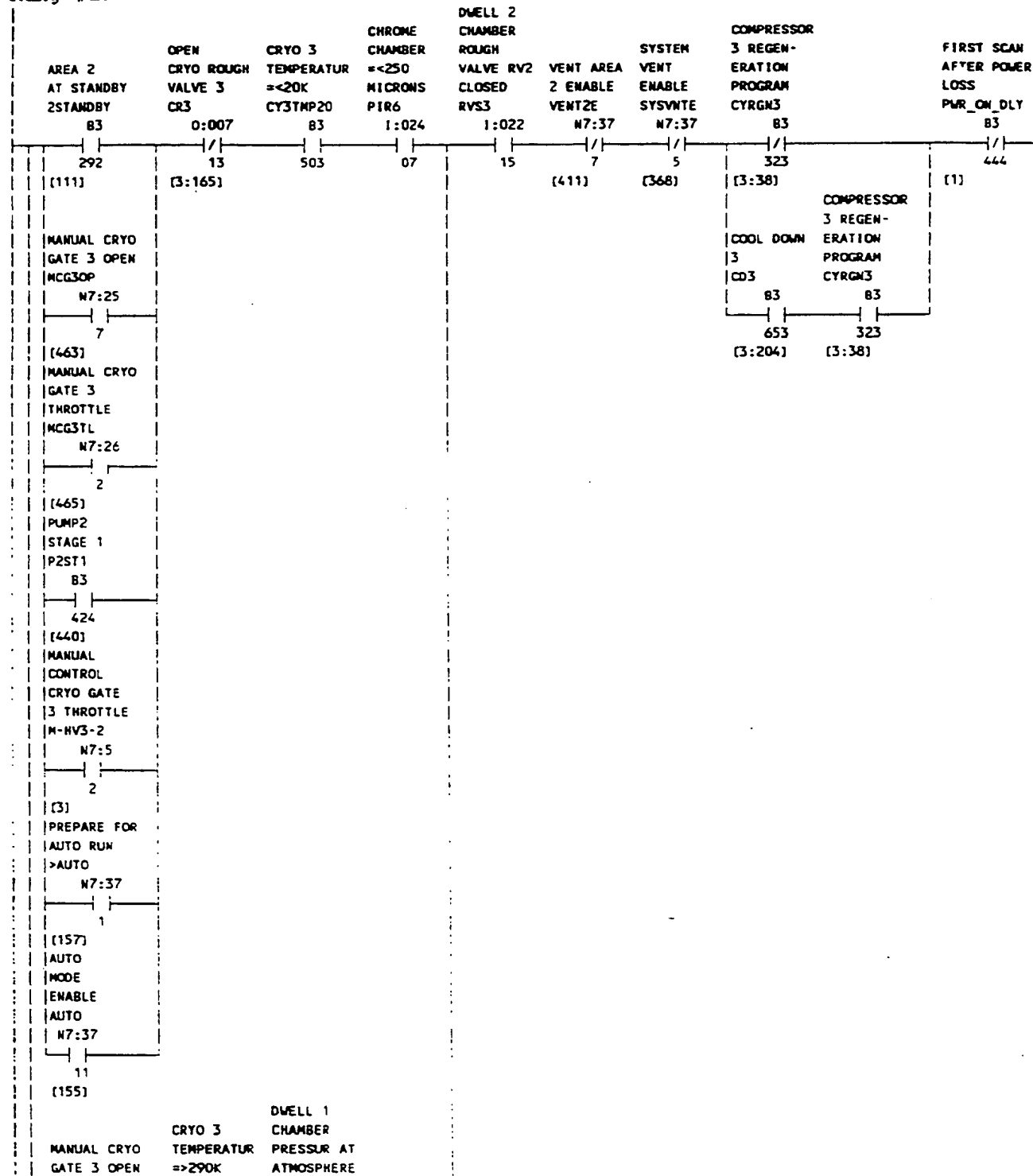
182

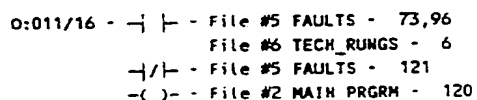
Rung #119



0:011/15 - File #5 FAULTS - 73
 File #6 TECH_RUNGS - 6
 -|/| - File #5 FAULTS - 96,121
 -() - File #2 MAIN_PRGRM - 119

Rung #120





Rung #121

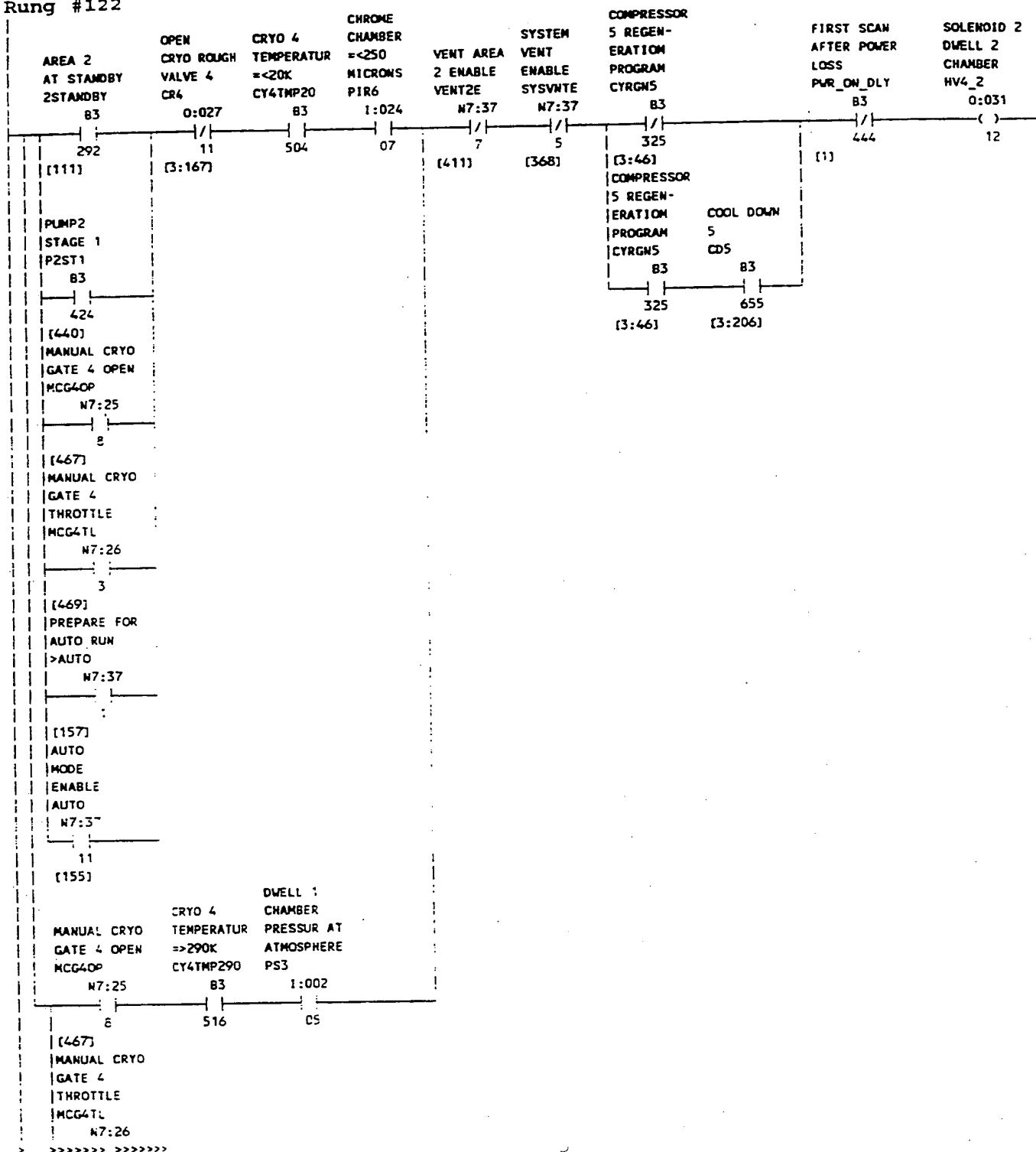


185

SOLENOID 1
DWELL 2
CHAMBER
HV4_1
0:031
____()____
11

0:031/11 - | | - File #5 FAULTS - 75
 File #6 TECH_RUNGS - 6
 -|/| - File #5 FAULTS - 98,123
 -() - File #2 MAIN_PRGRM - 121

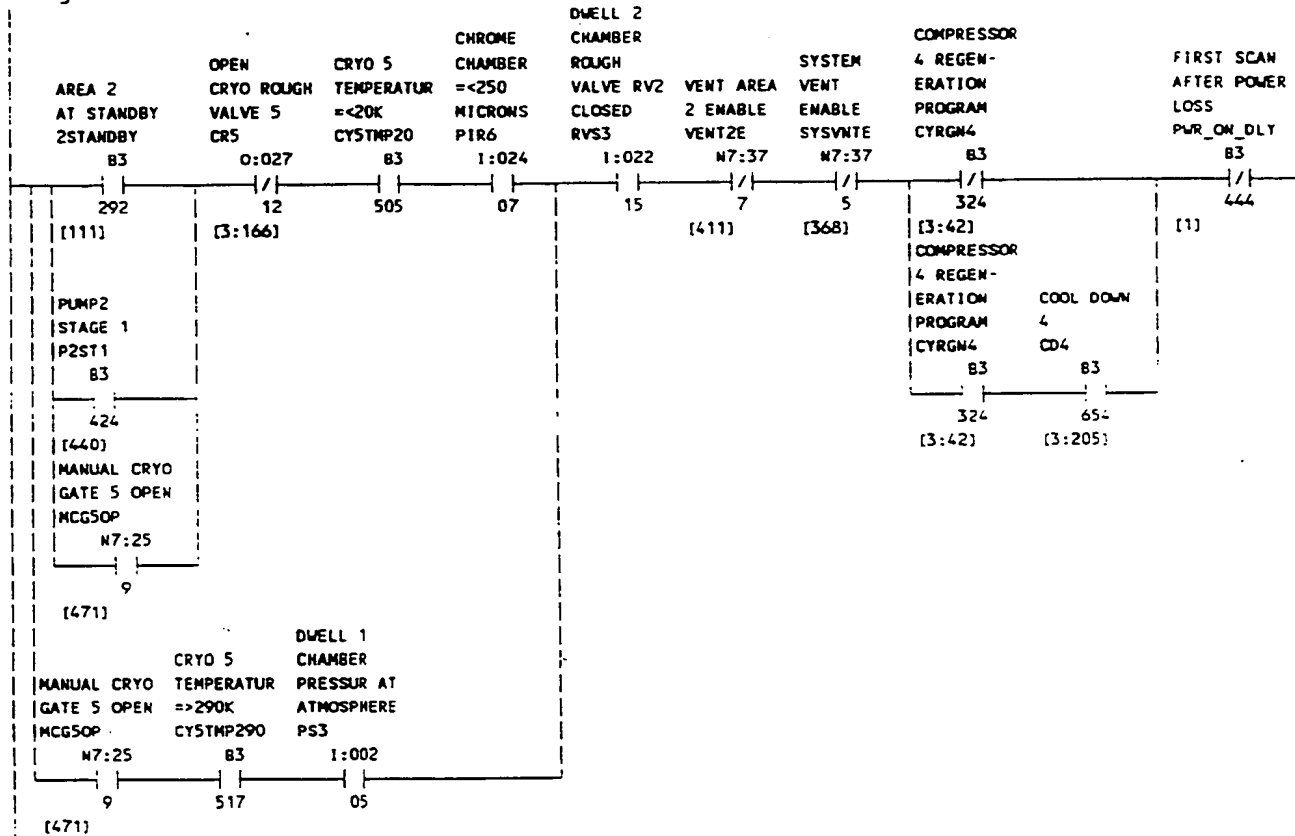
Rung #122



< <<<<< <<<<<<
3
[469]

0:031/12 - | | - File #5 FAULTS - 75,98
File #6 TECH_RUNGS - 6
-|/| - File #5 FAULTS - 123
-() - File #2 MAIN_PRGRM - 122

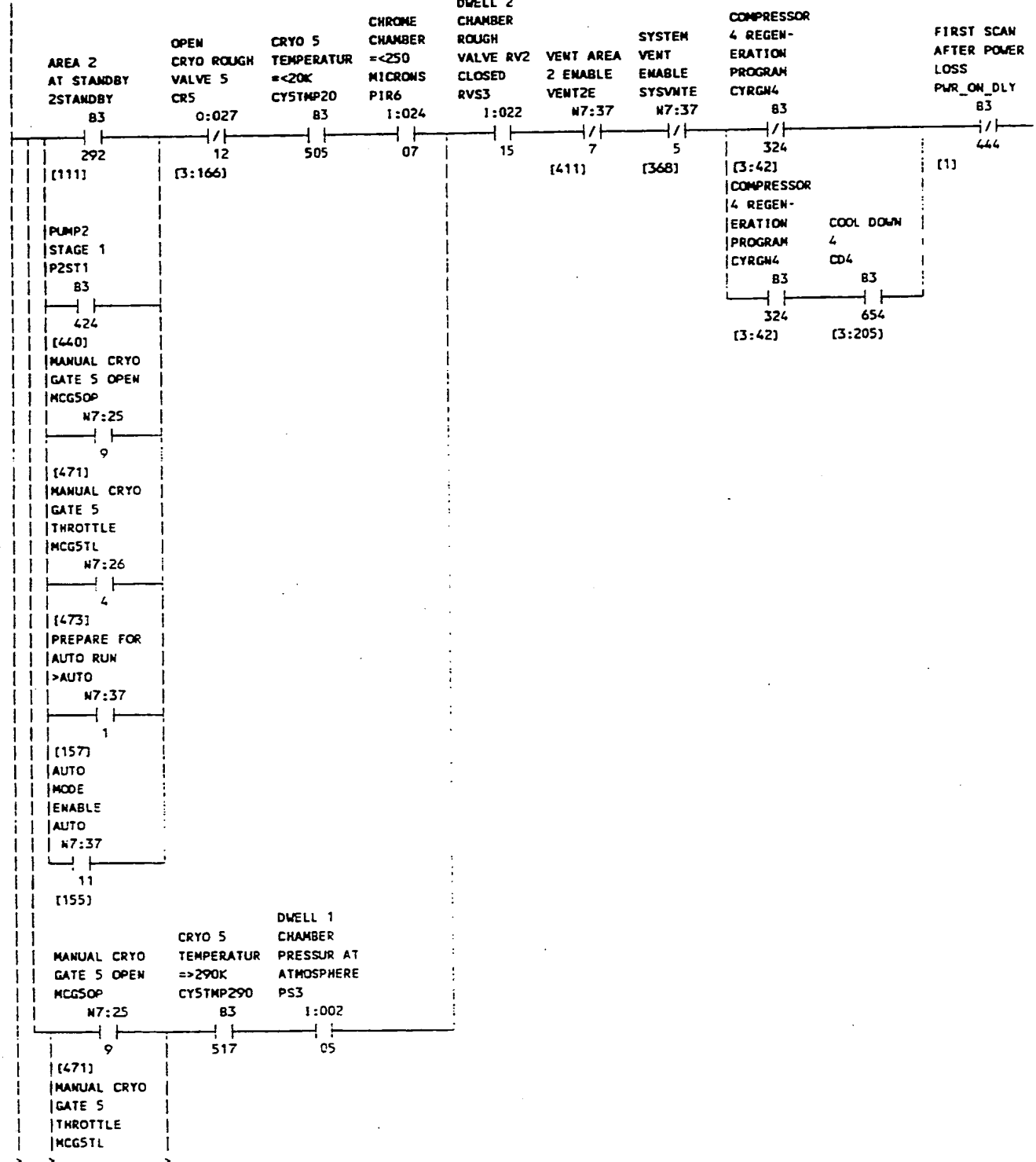
Rung #123

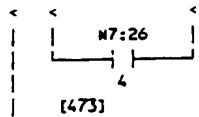


CRYO GATE
SOLENOID 1
HEATER 2
CHAMBER
HV5_1
0:031
-()
13

0:031/13 - | | - File #5 FAULTS - 77
File #6 TECH_RUNGS - 6
-|/| - File #5 FAULTS - 100,125
-() - File #2 MAIN_PRGRM - 123

Rung #124

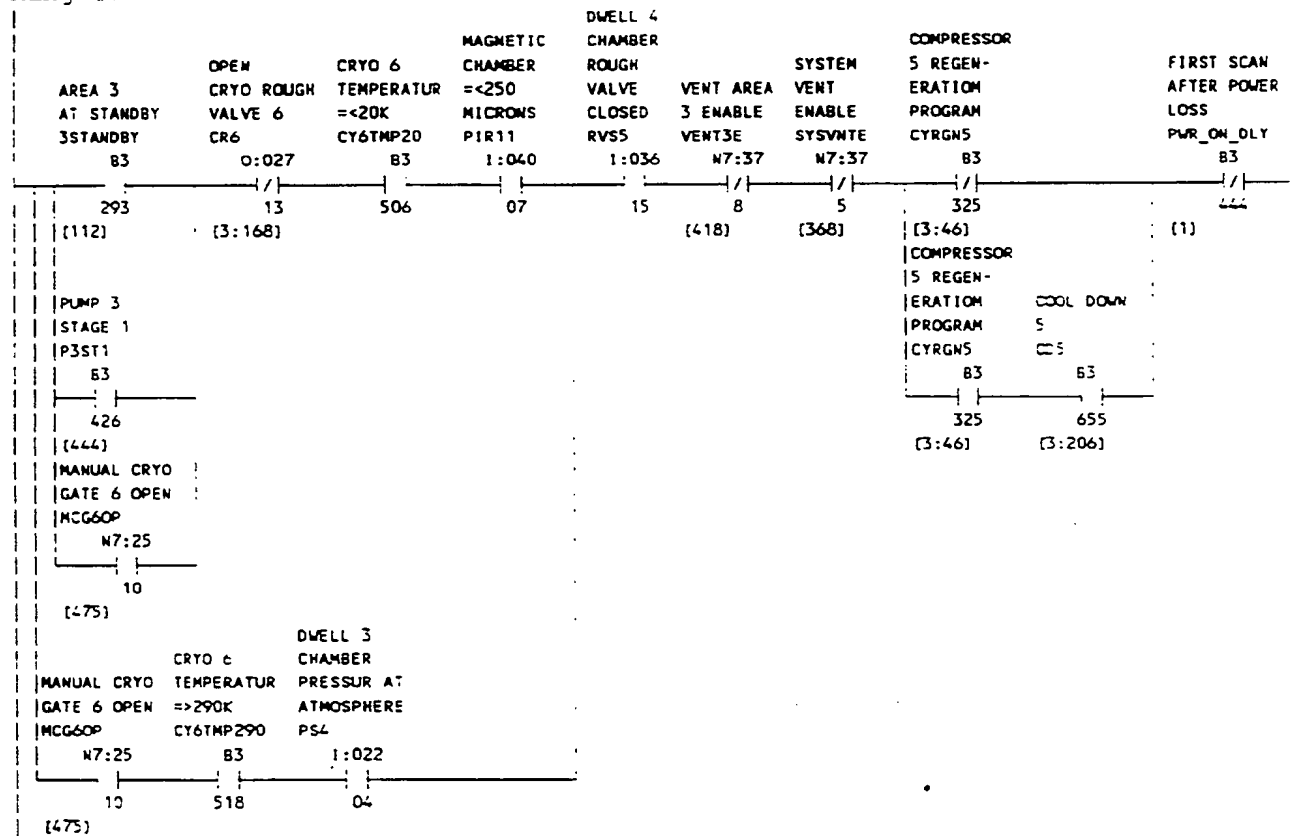




CRYO GATE
SOLENOID 2
HEATER 2
CHAMBER
HVS_2
0:031
()
14

0:031/14 - | | - File #5 FAULTS - 77,100
File #6 TECH_RUNGS - 6
| | - File #5 FAULTS - 125
- () - File #2 MAIN_PRGRM - 124

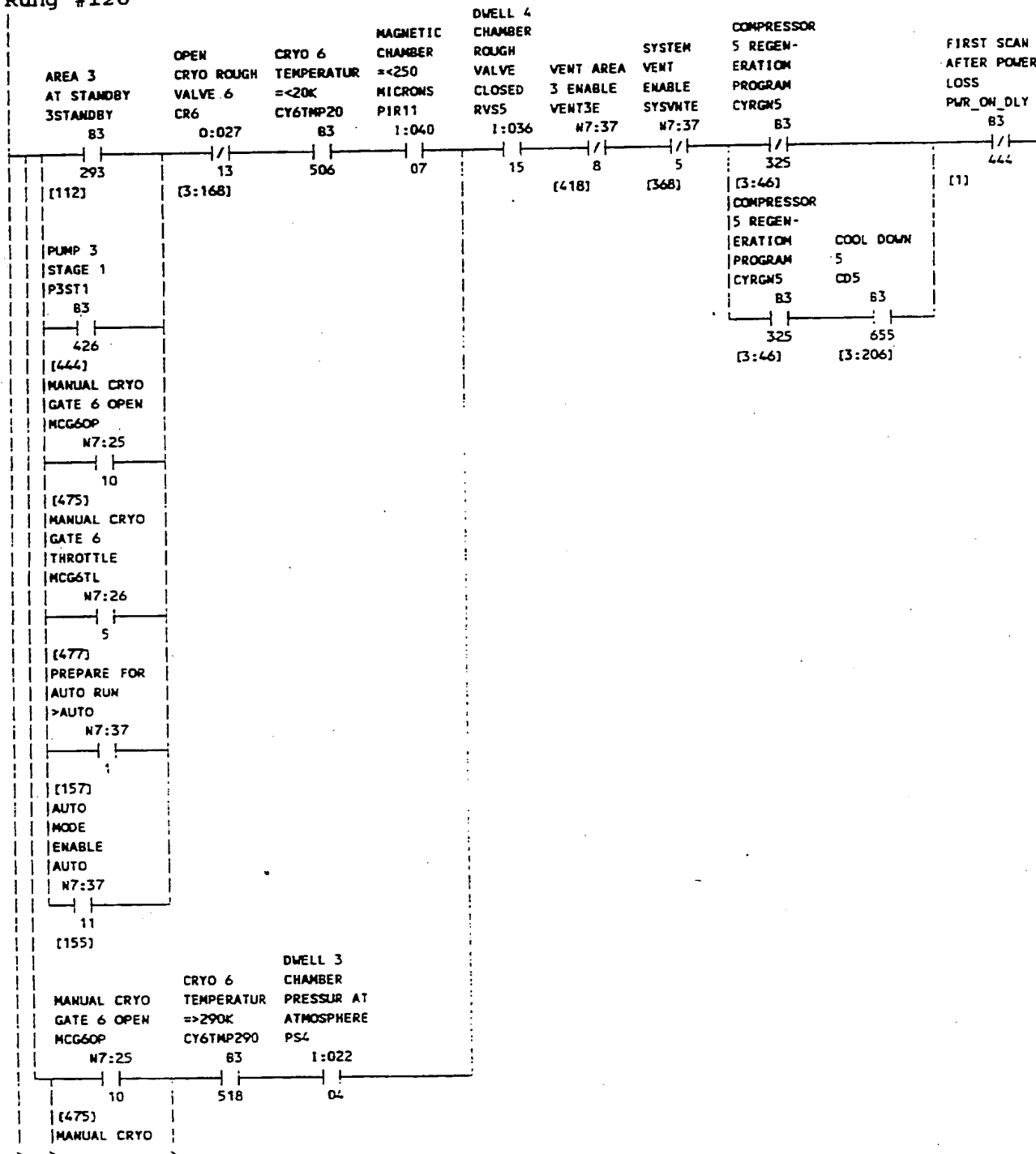
Rung #125

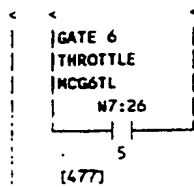


CRYO GATE
SOLENOID 1
DWELL 3
CHAMBER
HV6_1
0:031
()
15

0:031/15 - | | - File #5 FAULTS - 77

File #6 TECH_RUNG 6
 - File #5 FAULTS - 127
 - File #2 MAIN_PRGRM - 125
 Rung #126

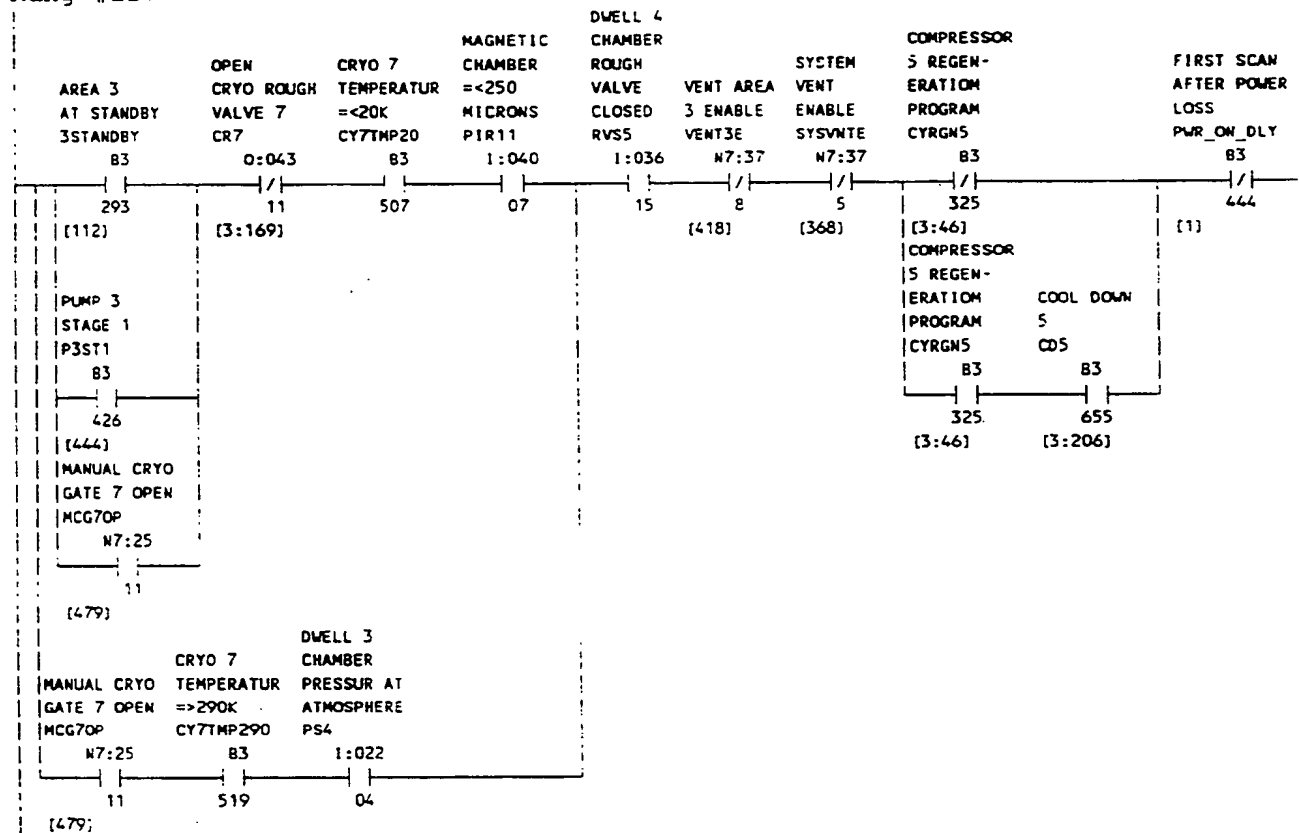




CRYO GATE
SOLENOID 2
DWELL 3
CHAMBER
HV6_2
0:031
()
16

0:031/16 - | | - File #5 FAULTS - 79,102
File #6 TECH_RUNGS - 6
- | | - File #5 FAULTS - 127
- () - File #2 MAIN_PRGRM - 126

Rung #127

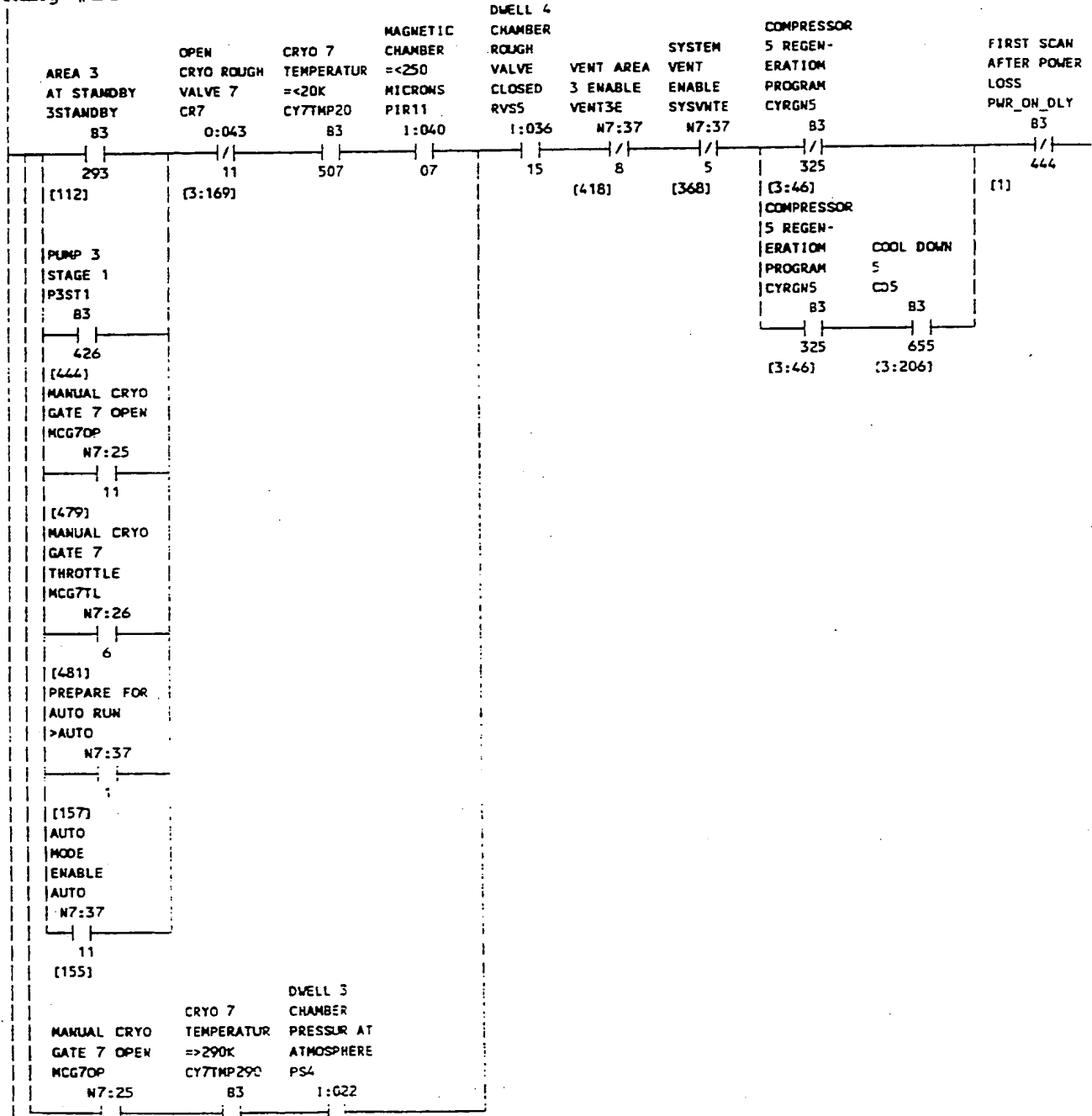


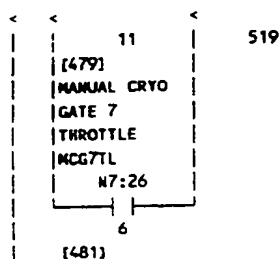
CRYO GATE
SOLENOID 1
DWELL 4
CHAMBER
HV7_1
0:045
()

192

0:045/11 - | | - File #5 FAULTS - 81
 File #6 TECH_RUNGS - 6
 -|/| - File #5 FAULTS - 104,129
 -| - File #2 MAIN_PRGRM - 127

Rung #128





CRYO GATE
SOLENOID 2
DWELL 4
CHAMBER
MV7_2
0:045
— () —
12

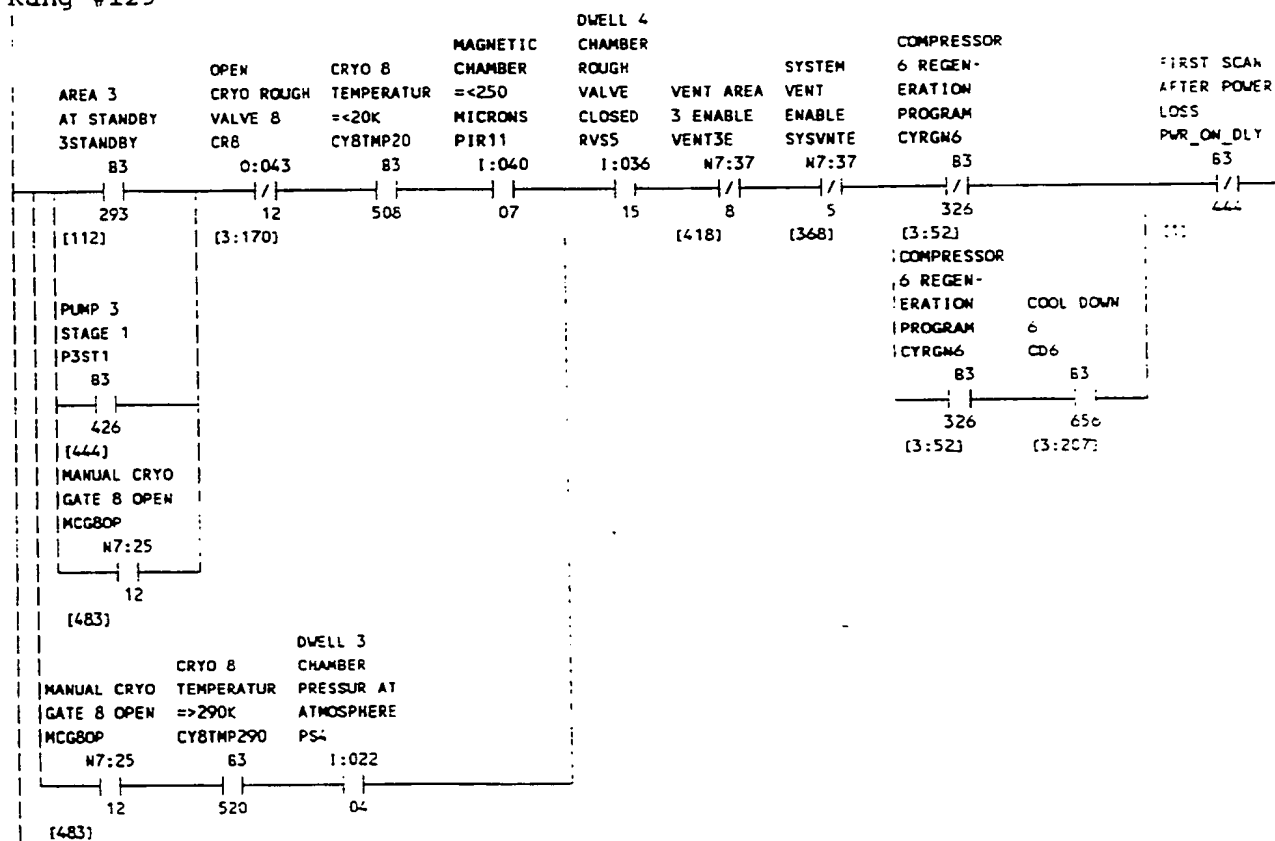
0:045/12 - | | - File #5 FAULTS - 81,104

File #6 TECH_RUNGS - 7

| | - File #5 FAULTS - 129

- () - File #2 MAIN_PRGRM - 128

Rung #129

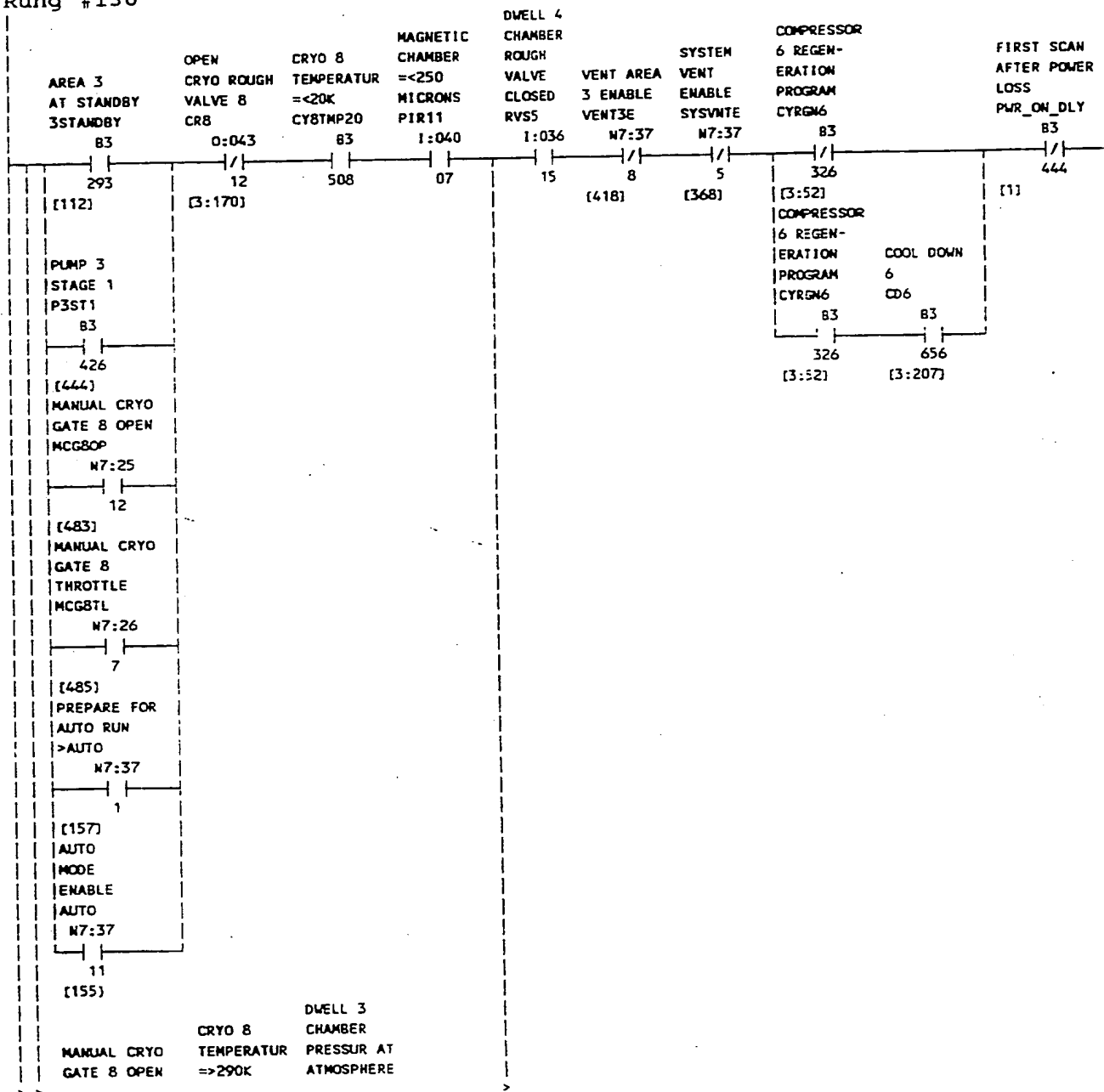


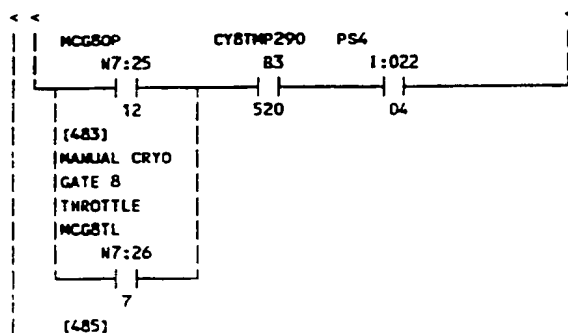
CRYO GATE
SOLENOID 1
BUFFER 3
CHAMBER

194

HV8_1
0:045
13

0:045/13 - | | - File #5 FAULTS - 83
File #6 TECH_RUNGS - 7
| | - File #5 FAULTS - 106,131
- () - File #2 MAIN_PRGRM - 129
Rung #130

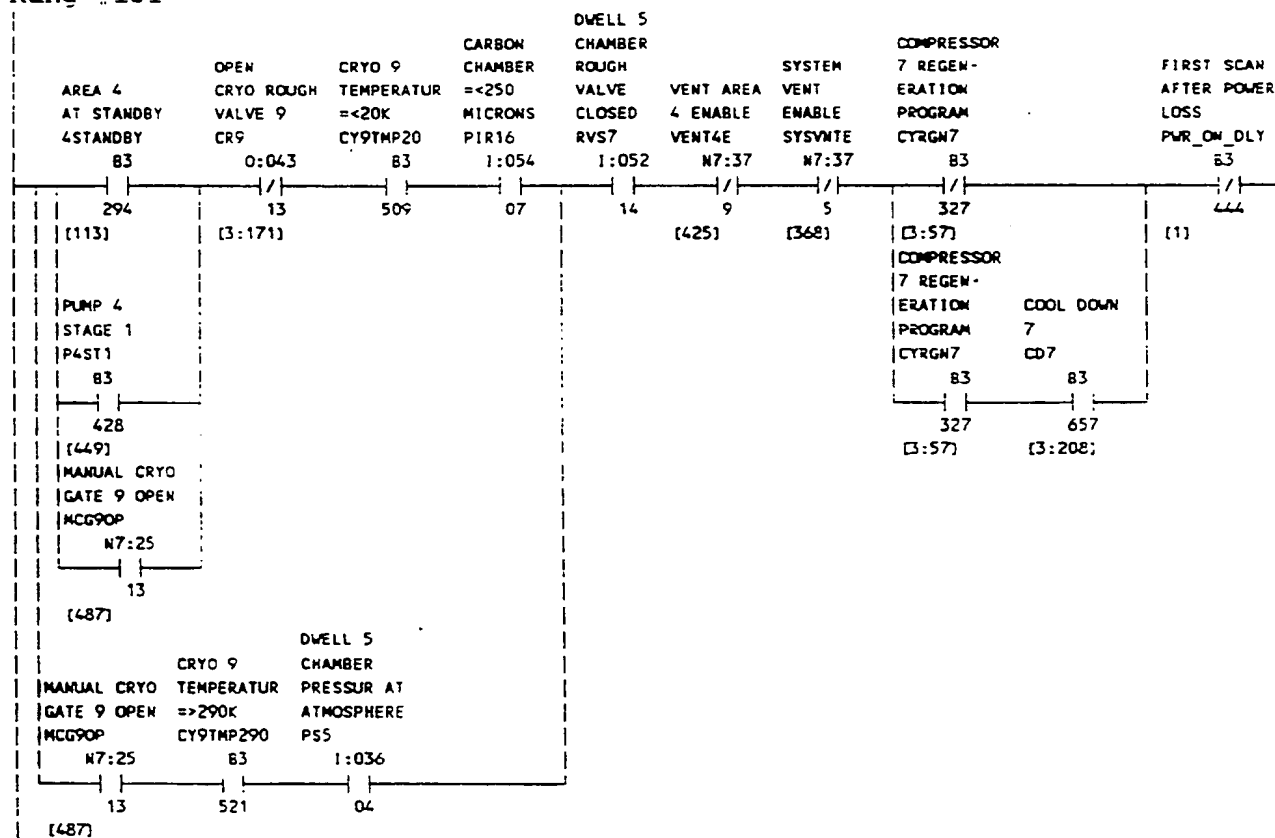




CRYO GATE
SOLENOID 2
BUFFER 3
CHAMBER
NV8_2
0:045
()
14

0:045/14 - | - File #5 FAULTS - 83,106
File #6 TECH_RUNGS - 7
-|/| - File #5 FAULTS - 131
-() - File #2 MAIN_PRGRM - 130

Rung #131



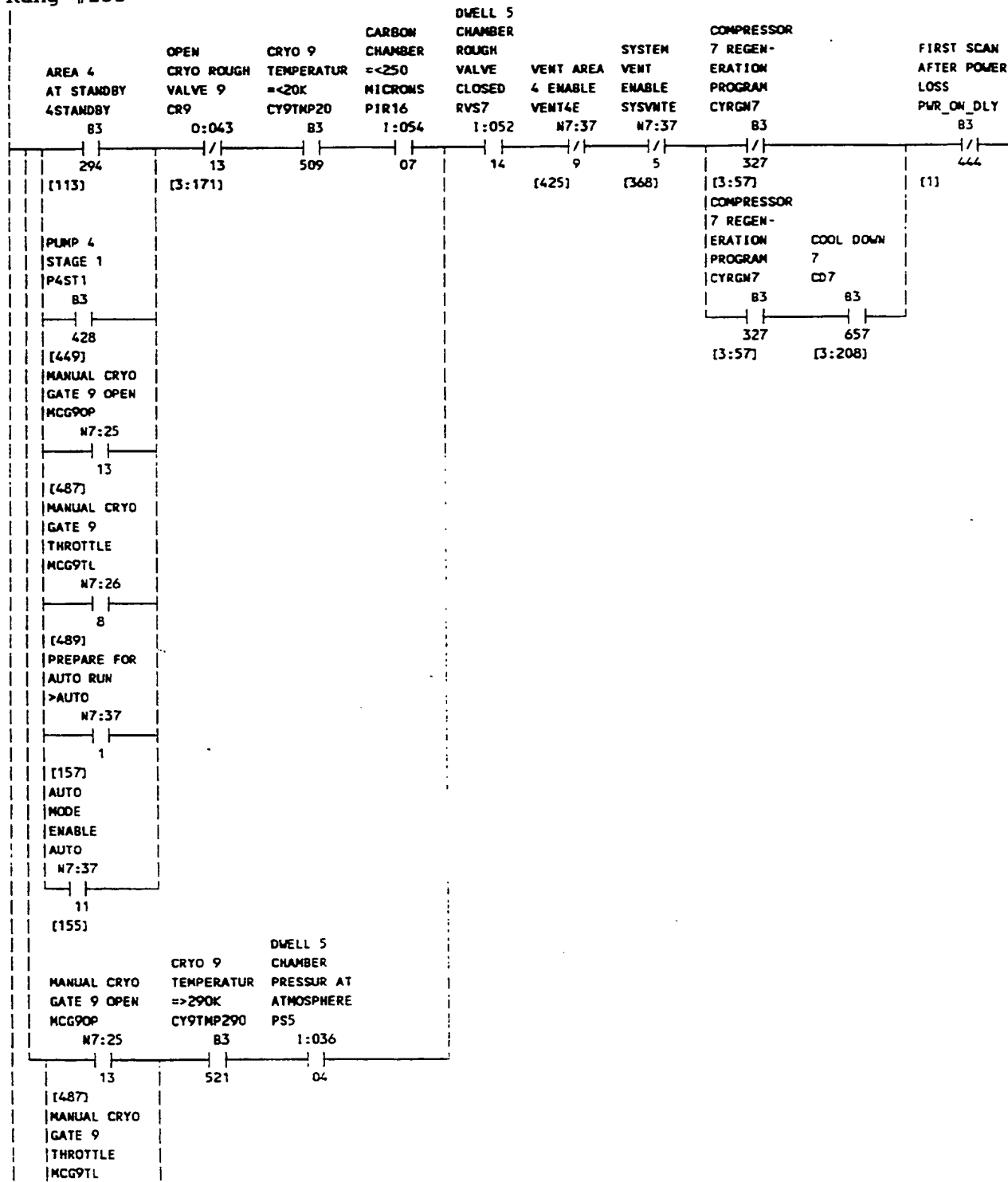
CRYO GATE

196

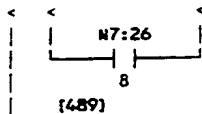
SOLENOID 1
DWELL 5
CHAMBER
HV9_1
0:045
— () —
15

0:045/15 - | | - File #5 FAULTS - 85
File #6 TECH_RUNGS - 7
-|/| - File #5 FAULTS - 108,133
-() - File #2 MAIN_PRGRM - 131

Rung #132



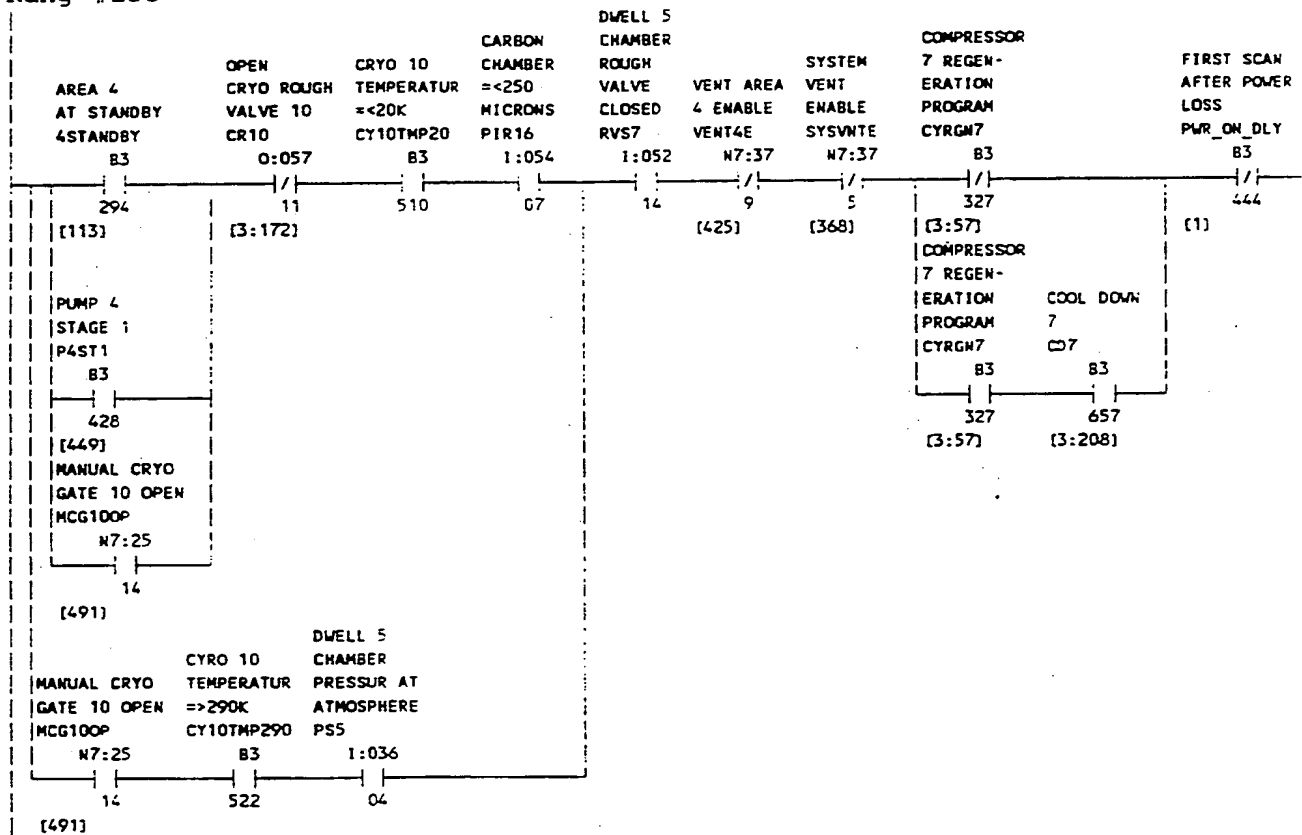
198



CRYO GATE
SOLENOID 2
DWELL 5
CHAMBER
HV9_2
0:045
()
16

0:045/16 - | | - File #5 FAULTS - 85,108
File #6 TECH_RUNGS - 7
- | | - File #5 FAULTS - 133
- () - File #2 MATH_PRGRM - 132

Rung #133



CRYO GATE
SOLENOID 1
DWELL 6
CHAMBER
HV10_1
0:061
()
11

0:061/11 - | | - File #5 FAULTS - 87,110

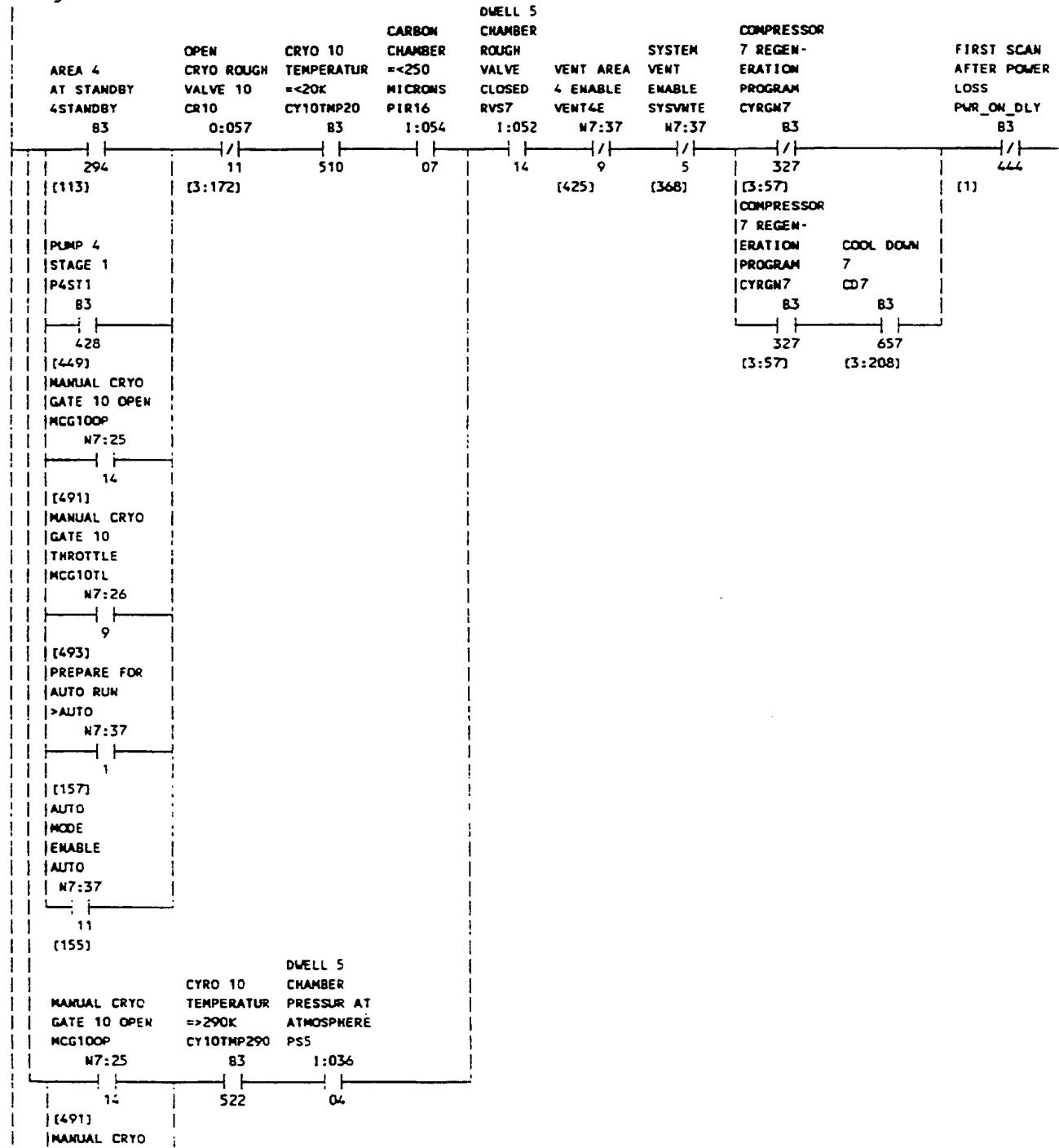
199

File #6 TECH_RUNG. 7

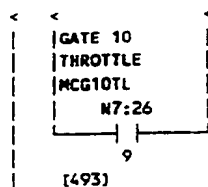
-|/- File #5 FAULTS - 135

-() - File #2 MAIN_PRGRM - 133

Rung #134



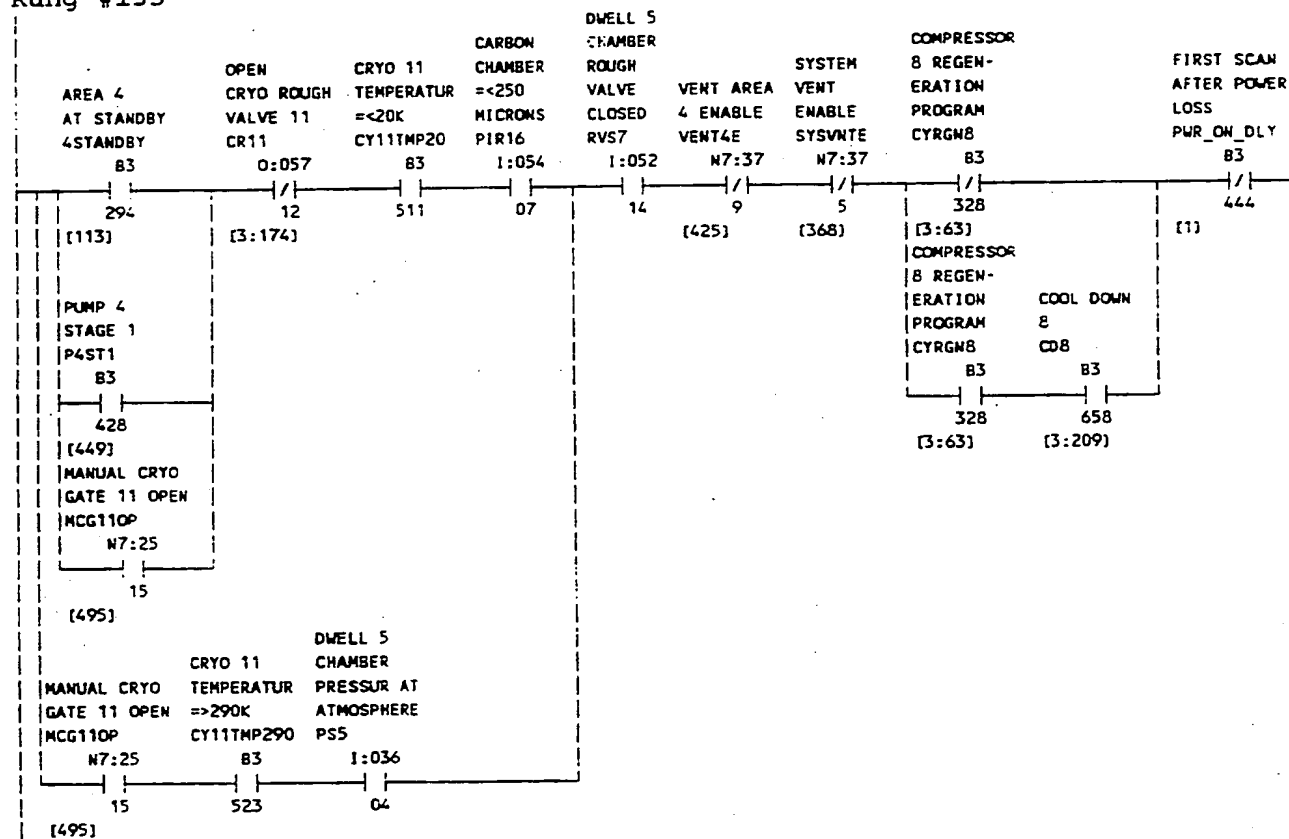
200



CRYO GATE
 SOLENOID 2
 DWELL 6
 CHAMBER
 HV10_2
 0:061
 ()
 12

0:061/12 - | | - File #5 FAULTS - 87
 File #6 TECH_RUNGS - 7
 | | - File #5 FAULTS - 110,135
 - () - File #2 MATH_PRGRM - 134

Rung #135



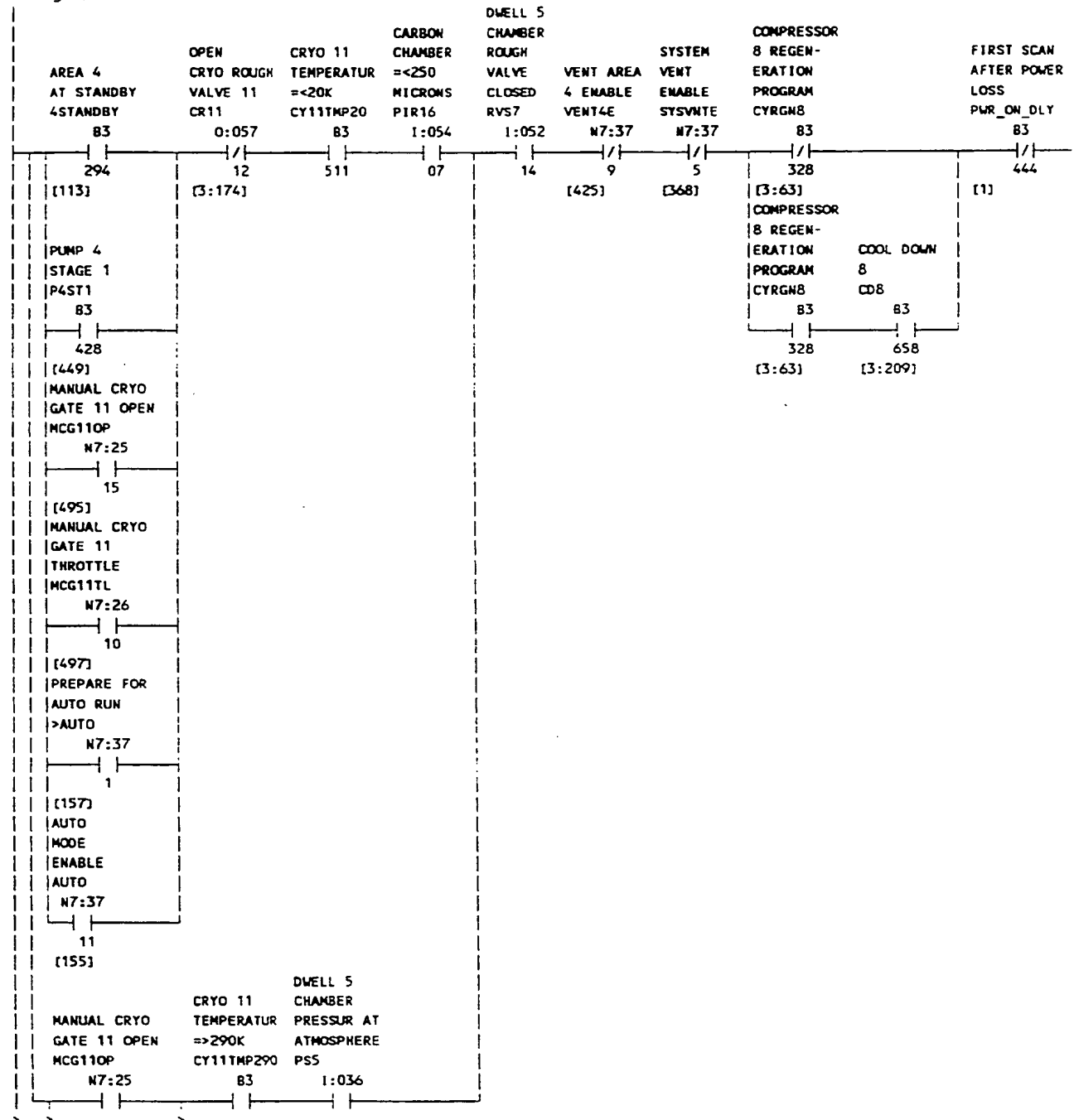
CRYO GATE
 SOLENOID 1
 BUFFER 4
 CHAMBER
 HV11_1
 0:061
 ()

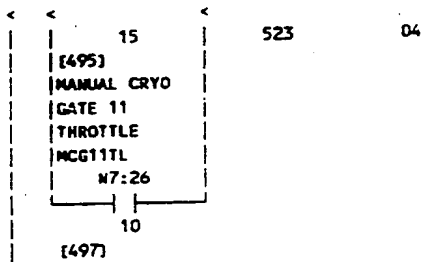
201

13

0:061/13 - | | - File #5 FAULTS - 89
 File #6 TECH_RUNGS - 7
 -|/| - File #5 FAULTS - 112,137
 -() - File #2 MAIN_PRGRM - 135

Rung #136

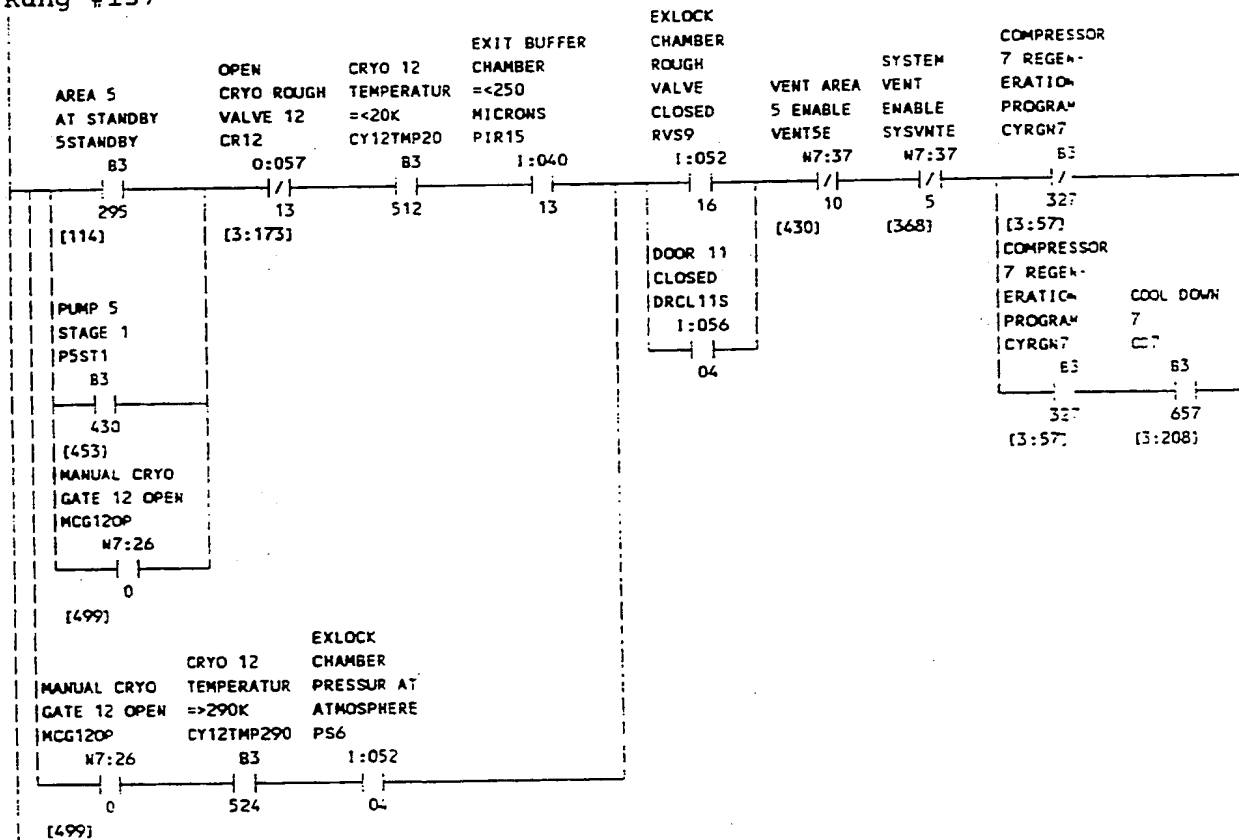




CRYO GATE
SOLENOID 2
BUFFER 4
CHAMBER
HV11_2
0:061
()
14

0:061/14 - | | - File #5 FAULTS - 89,112
File #6 TECH_RUNGS - 7
-|/| - File #5 FAULTS - 137
-() - File #2 MAIN_PRGRM - 136

Rung #137

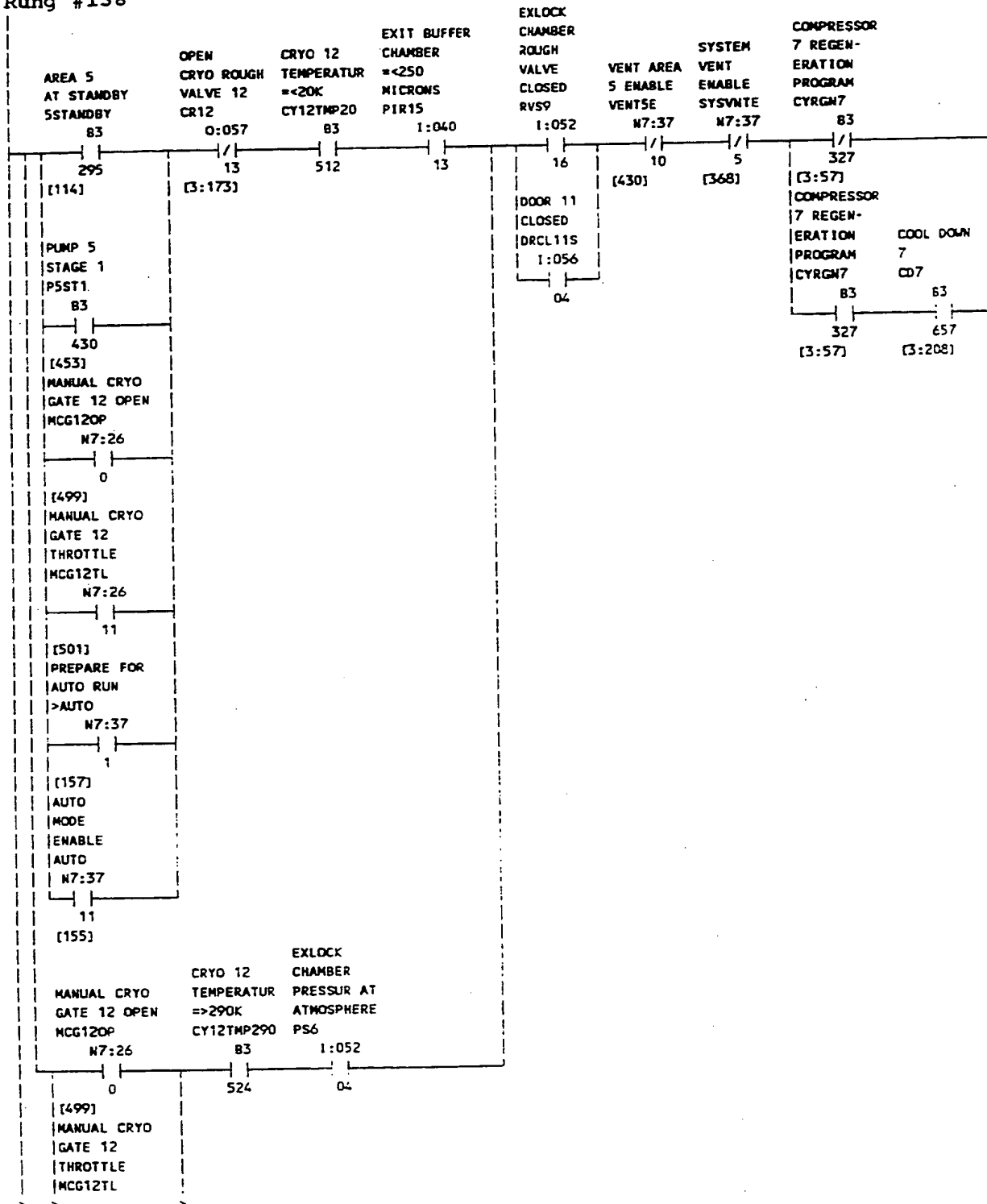


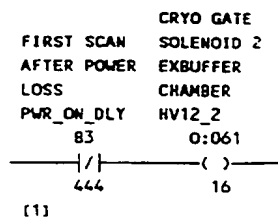
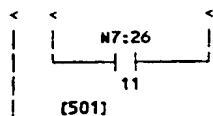
CRYO GATE
SOLENOID 1
FIRST SCAN
AFTER POWER
LOSS
EXBUFFER
CHAMBER

0:061/15 - | | - File #5 FAULTS - 91
 File #6 TECH_RUNGS - 7
 -|/| - File #5 FAULTS - 114,139
 - () - File #2 MAIN_PRGRM - 137

PWR_ON_DLY	HV12_1
83	0:061
/	()
444	15
[1]	

Rung #138





0:061/16 - | | - File #5 FAULTS - 91,114
 File #6 TECH_RUNGS - 7
 -|/| - File #5 FAULTS - 139
 -() - File #2 MAIN_PRGRM - 138

Rung #139

| DOOR 10
 | CLOSED
 | DRCL10S
 | 1:056
 | 02

EXITLOCK
 NIVAC BAFFLE
 ENABLE
 HV12_3
 0:061
 (U)
 17

0:061/17 - -(L) - File #2 MAIN_PRGRM - 324
 -(U) - File #2 MAIN_PRGRM - 139

Rung #140

	HEATER 1	CHROME	MAGNETIC	CARBON	EXIT BUFFER
PUMPDOWN	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER
SYSTEM	=<250	=<250	=<250	=<250	=<250
ENABLE	MICRONS	MICRONS	MICRONS	MICRONS	MICRONS
PDSE	PIR2	PIR6	PIR11	PIR16	PIR15
	83	1:004	1:024	1:040	1:054
	303	10	07	07	13

SYSTEM IS
 PUMPED
 DOWN
 SYS_PD
 83
 389

[23]
 83/389 - | | - File #2 MAIN_PRGRM - 22
 -() - File #2 MAIN_PRGRM - 140

Rung #141

| HEATER
 | SHIELD H2O
 | FLOW
 | SWITCH 1
 | HSFS1
 | 1:006
 | 10

HEATER SHIELD
 FLOW SWITCH
 1 SENSOR
 TIMER
 HSFS1TMR
 TOF
 TIMER OFF DELAY (EW)
 TIMER: T4:191
 BASE (SEC): 1.0 (DN)
 PRESET: 20
 ACCUM: 0

T4:191.DN - | | - File #2 MAIN_PRGRM - 147
 -|/| - File #2 MAIN_PRGRM - 149

Rung #142

HEATER
SHIELD H20
FLOW
SWITCH 2
HSFS2

1:006

11

T4:192.DN - | | - File #2 MATH_PRGRM - 147
-|/| - File #2 MATH_PRGRM - 149

HEATER SHIELD
FLOW SWITCH
2 SENSOR
HSFS2TMR

TOF
TIMER OFF DELAY (EN)
TIMER: T4:192
BASE (SEC): 1.0 (DN)
PRESET: 20
ACCUM: 0

Rung #143

HEATER
SHIELD H20
FLOW
SWITCH 3
HSFS3

1:006

12

T4:193.DN - | | - File #2 MATH_PRGRM - 148
-|/| - File #2 MATH_PRGRM - 150

HEATER SHIELD
FLOW SWITCH
3 TIMER
HSFS3TMR

TOF
TIMER OFF DELAY (EN)
TIMER: T4:193
BASE (SEC): 1.0 (DN)
PRESET: 20
ACCUM: 0

Rung #144

HEATER
SHIELD H20
FLOW
SWITCH 4
HSFS4

1:006

13

T4:194.DN - | | - File #2 MATH_PRGRM - 148
-|/| - File #2 MATH_PRGRM - 150

HEATER SHIELD
FLOW SWITCH
4 TIMER
HSFS4TMR

TOF
TIMER OFF DELAY (EN)
TIMER: T4:194
BASE (SEC): 1.0 (DN)
PRESET: 20
ACCUM: 0

Rung #145

HEATER
SHIELD H20
FLOW
SWITCH 5
HSFS5

1:023

16

HEATER SHIELD
FLOW SWITCH
5 TIMER
HSFS5TMR

TOF
TIMER OFF DELAY (EN)
TIMER: T4:195
BASE (SEC): 1.0 (DN)
PRESET: 20
ACCUM: 20

Rung #146

HEATER
SHIELD H2O
FLOW
SWITCH 6
HSFS6

1:023

17

HEATER SHIELD
FLOW SWITCH
6 TIMER
HSFS6TMR

TOF	
TIMER OFF DELAY	(EN)
TIMER:	T4:196
BASE (SEC):	1.0 (DN)
PRESET:	20
ACCUM:	20

Rung #147

RUN HEATER
GROUP 1
TS26
N7:17

HEATER 1
CHAMBER
HEATER = <250
ALARM MICRONS
PIR2
1:004

HEATER WATER VALVE 1
HH201
0:010

HEATER WATER VALVE 2
HH202
0:010

SUBSTRATE
HEATER 1A
ON
RH1A
0:046

2	DN	DN	530	10	16	17	(L)	10
[3]	[141]	[142]			[737]	[736]		

0:046/10 - (U) - File #2 MAIN_PRGRM - 153
 (U) - File #2 MAIN_PRGRM - 149
 0:046/11 - (U) - File #2 MAIN_PRGRM - 153
 (U) - File #2 MAIN_PRGRM - 149
 0:046/15 - (U) - File #2 MAIN_PRGRM - 149
 0:046/16 - (U) - File #2 MAIN_PRGRM - 149
 N7:38/2 - (U) - File #2 MAIN_PRGRM - 149
 F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2
 N7:38/5 - (L) - File #2 MAIN_PRGRM - 149
 F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2

SUBSTRATE
HEATER 1B
ON
RH1B
0:046

(L)
11

SUBSTRATE
HEATER 3A
ON
RH3A
0:046

(L)
15

SUBSTRATE
HEATER 3B
ON
RH3B
0:046

(L)
16

MANUAL
RUN HEATER
GROUP 1
MRNG1
N7:38
(L)

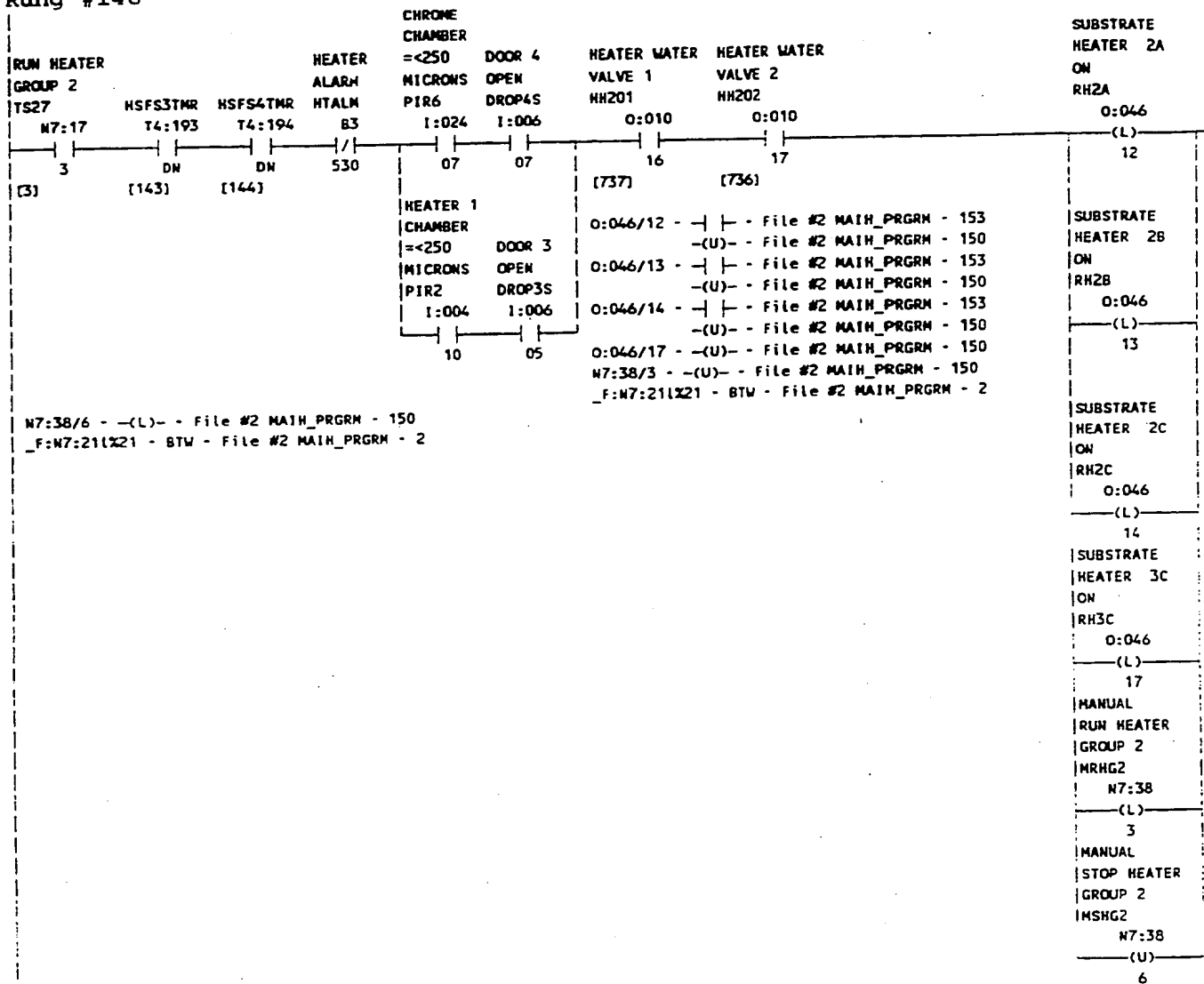
2

MANUAL
STOP HEATER
GROUP 1
MSHG1
N7:38
(U)

5

208

Rung #148



Rung #149

STOP HEATER
GROUP 1
TS29

N7:17

5

[3]

O:046/10 - | | - File #2 MAIN_PRGRM - 153
-(L)- - File #2 MAIN_PRGRM - 147
O:046/11 - | | - File #2 MAIN_PRGRM - 153
-(L)- - File #2 MAIN_PRGRM - 147
O:046/15 - -(L)- - File #2 MAIN_PRGRM - 147
O:046/16 - -(L)- - File #2 MAIN_PRGRM - 147
N7:38/2 - -(L)- - File #2 MAIN_PRGRM - 147
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:38/5 - -(U)- - File #2 MAIN_PRGRM - 147
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

HSFS1TMR
T4:191

|/|

DN

[141]

HSFS2TMR
T4:192

|/|

DN

[142]

HEATER
ALARM
HTALM

B3

530

HEATER WATER
VALVE 2
HH202

O:010

|/|

17

[736]

HEATER WATER
VALVE 1
HH201

O:010

|/|

16

[737]

AUTO OFF
PULSE
AUOFFPULSE

SUBSTRATE
HEATER 1A
ON
RH1A
O:046

(U)

10

SUBSTRATE
HEATER 1B
ON
RH1B
O:046

(U)

11

SUBSTRATE
HEATER 3A
ON
RH3A
O:046

(U)

15

SUBSTRATE
HEATER 3B
ON
RH3B
O:046

(U)

16

MANUAL
RUN HEATER
GROUP 1
MRHG1
N7:38

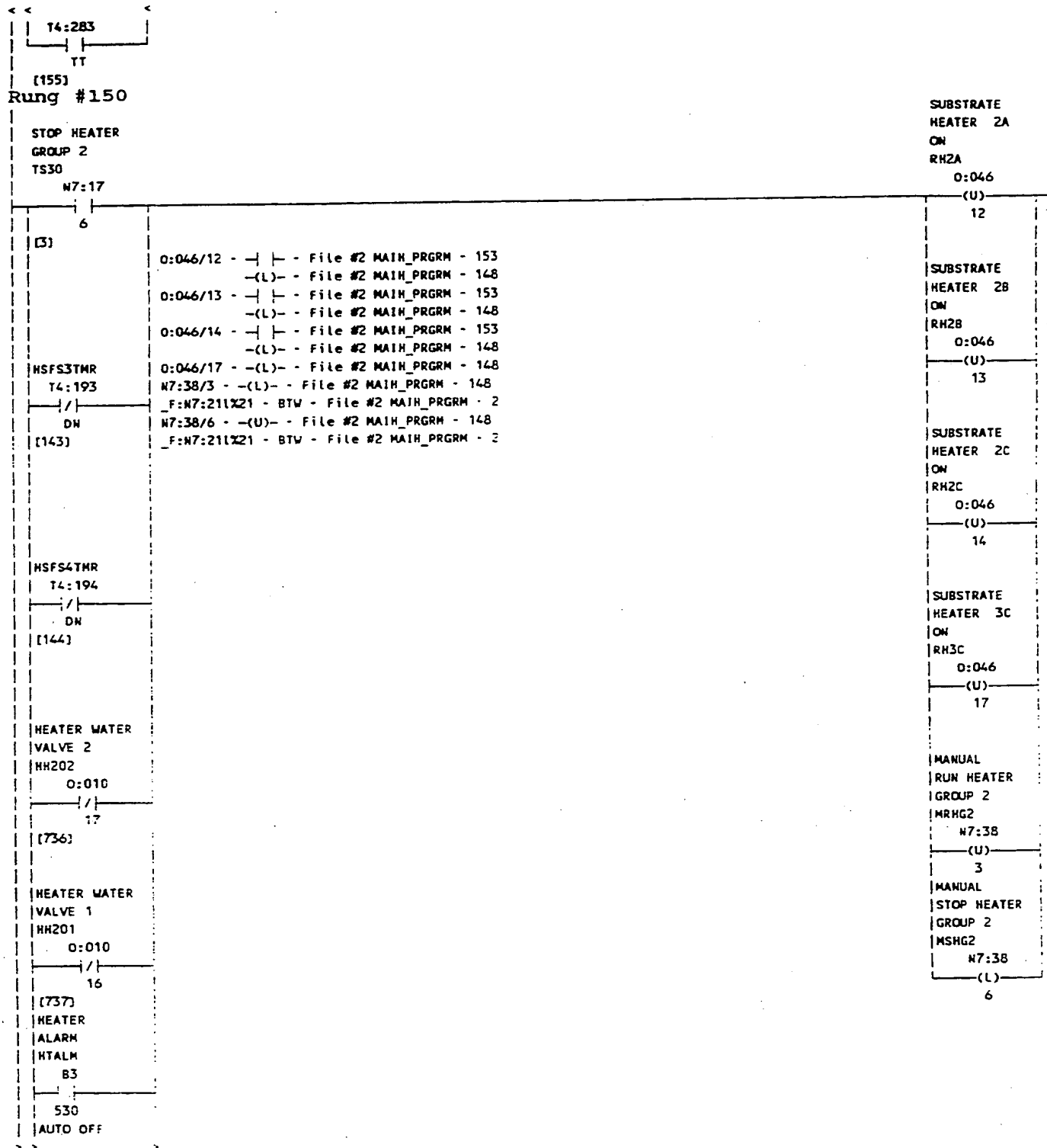
(U)

2

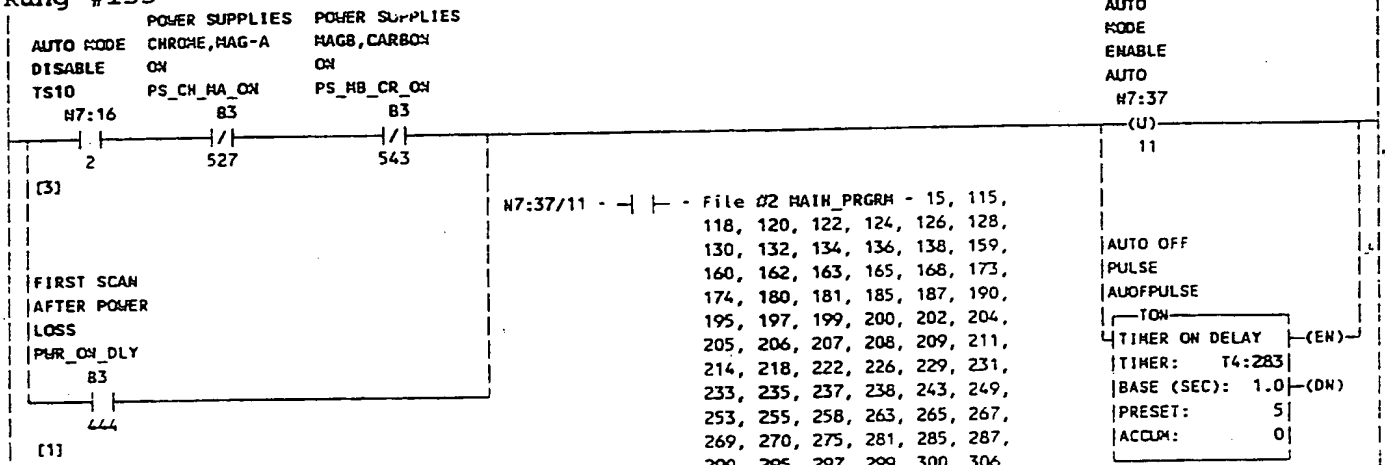
MANUAL
STOP HEATER
GROUP 1
MSHG1
N7:38

(L)

5



Rung #155



310, 312, 315, 320, 324, 327, 331, 335, 337, 338, 341, 346, 347, 351, 355, 614, 616, 624, 625, 630, 631, 633

File #5 FAULTS - 0, 1, 2, 3, 4, 5, 6, 7, 8, 9, 10, 11, 12, 13, 14

| | - File #2 MAIN_PRGRM - 84, 98, 104, 116, 187, 200, 212, 327, 369, 405, 411, 418, 425, 430, 674, 676, 684, 688, 690, 698

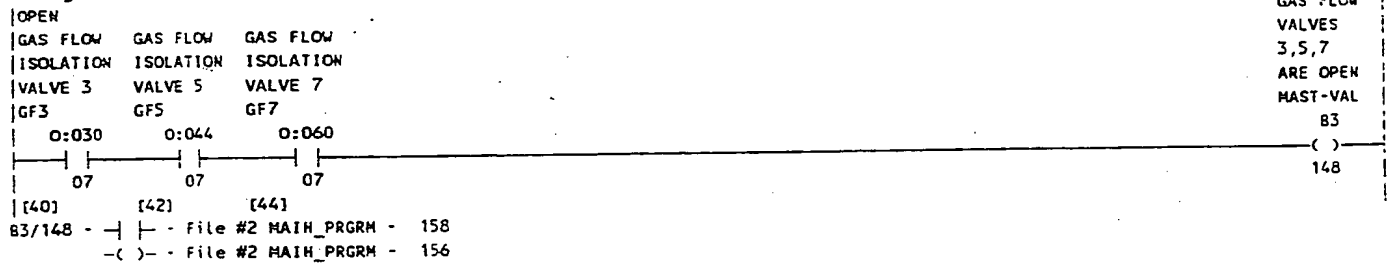
-(L)- File #2 MAIN_PRGRM - 158

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

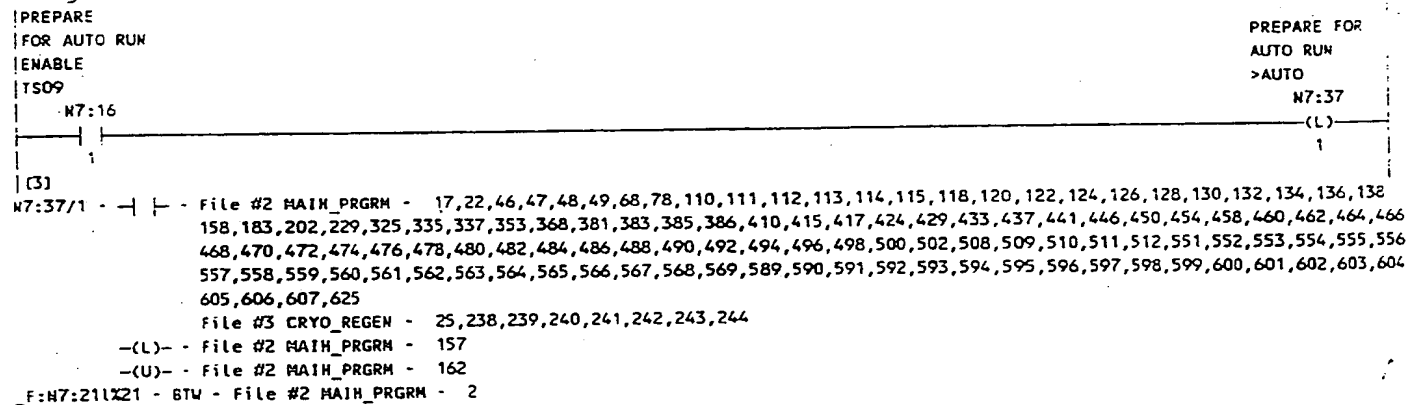
T4:283.DN - | | - File #2 MAIN_PRGRM - 711

T4:283.TT - | | - File #2 MAIN_PRGRM - 38, 39, 40, 41, 42, 44, 45, 84, 98, 105, 106, 107, 108, 109, 149, 150, 223, 237, 240, 243, 269, 272, 275

Rung #156



Rung #157



Rung #160

AUTO
MODE
ENABLE
AUTO
N7:37

RETURN CONVEYOR
OFF DELAY
RC_OFF

—TOP—
TIMER OFF DELAY —(EN)—
TIMER: T4:332
IBASE (SEC): 1.0 —(DN)
PRESET: 18001
ACCU: 01

11
[158]

T4:332.DN - —/— - File #2 MAIN_PRGRM - 161

MANUAL CONTROL
RETURN CONVEYOR
RTNCHVYR
1:055

03

Rung #161

RC_OFF
T4:332

RETURN CONVEYOR
ON
RTNCHVYR

0:060

DN
[160]

(11)

01

0:060/01 - —(L)— - File #2 MAIN_PRGRM - 159
—(U)— - File #2 MAIN_PRGRM - 161

Rung #162

AUTO MODE
DISABLE
TS10
N7:16

PREPARE FOR
AUTO RUN
>AUTO

N7:37

2
[3]

(U)

[3]

N7:37/1 - —/— - File #2 MAIN_PRGRM - 17, 22, 46, 47, 48, 49, 68, 78, 110, 111, 112, 113, 114, 115,
118, 120, 122, 124, 126, 128, 130, 132, 134, 136, 138, 158, 183, 202, 229, 325,
335, 337, 353, 368, 381, 383, 385, 386, 410, 415, 417, 424, 429, 433, 437, 441,
446, 450, 454, 458, 460, 462, 464, 466, 468, 470, 472, 474, 476, 478, 480, 482,
484, 486, 488, 490, 492, 494, 496, 498, 500, 502, 508, 509, 510, 511, 512, 551,
552, 553, 554, 555, 556, 557, 558, 559, 560, 561, 562, 563, 564, 565, 566, 567,
568, 569, 589, 590, 591, 592, 593, 594, 595, 596, 597, 598, 599, 600, 601, 602,
603, 604, 605, 606, 607, 625

N7:37

File #3 CRYO_REGEN - 25, 238, 239, 240, 241, 242, 243, 244

11

—(L)— - File #2 MAIN_PRGRM - 157

[158]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 1

Rung #163

AUTO PALLET
MODE DOOR 1 DOOR 2 DETECTED
ENABLE CLOSED CLOSED RIGHT SIDE
AUTO DRCL1S DRCL2S LOADLOCK
N7:37 1:006 1:006 1:003

SOFT
ROUGHING
TIME
SOFTUP

11 00 02 05

[158]

—TOP—
TIMER ON DELAY —(EN)—
TIMER: T4:981
IBASE (SEC): 1.0 —(DN)
IPRESET: 0
IACCU: 0

T4:98.DN - —/— - File #2 MAIN_PRGRM - 167

T4:98.TT - — - File #2 MAIN_PRGRM - 164

215

Rung #164

SOFRUF

T4:98

TT

[163]

Rung #165

AUTOPULSE

T4:282

TT

[158]

B3/287 - | | - File #2 MAIN_PRGRM - 167, 183
-(U)- - File #2 MAIN_PRGRM - 166

COMPUTER

AUTO SIGNAL FOR

MODE AUTO MODE

ENABLE OK

AUTO COMPAUTO

N7:37 N7:16

11

11

[158] [3]

Rung #166

VENT

LOAD LOCK

VNT_LL

N7:24

13

[674]

B3/287 - | | - File #2 MAIN_PRGRM - 167, 183
-(L)- - File #2 MAIN_PRGRM - 165

PUMP-VENT

CYCLE LOAD

LOCK

PD-VNT-LL

N7:24

14

[676]

AUTO MODE

DISABLE

TS10

N7:16

2

[3]

MECH PUMP
SOFT ROUGH
VALVE
SOFRUFVLV
O:030

()

00

LOADLOCK
AUTO
LL_AUTO
B3

(L)

287

LOADLOCK
AUTO
LL_AUTO
B3

(U)

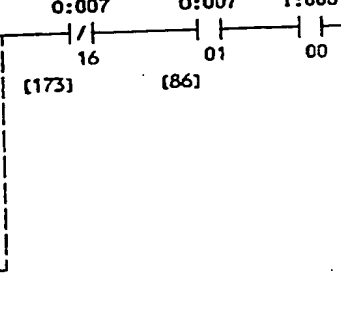
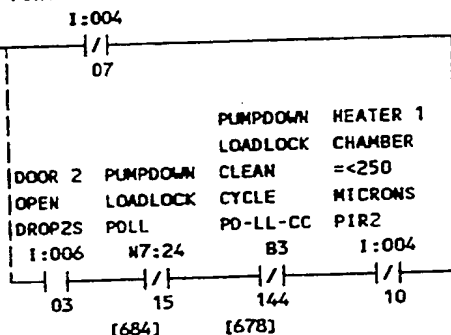
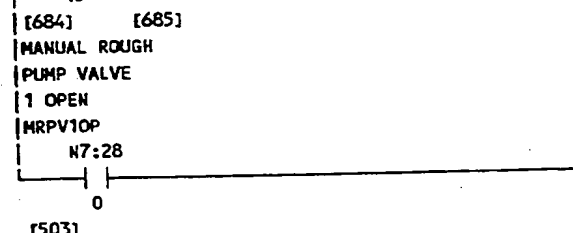
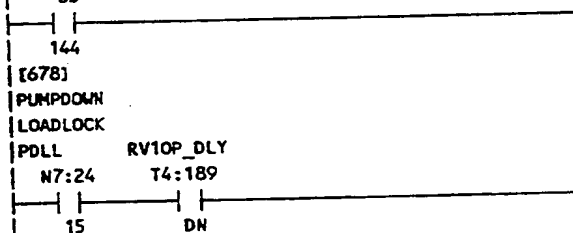
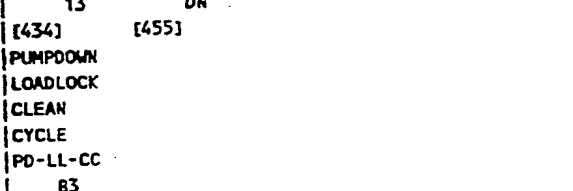
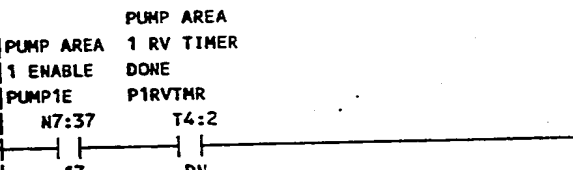
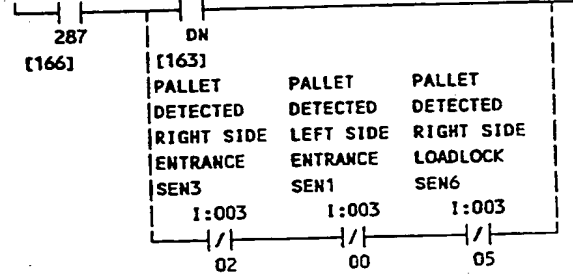
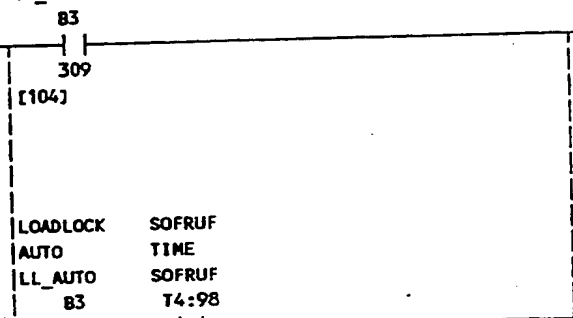
287

Rung #167

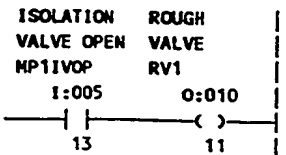
OPEN
ROUGHING
VALVES
1->5
OP_RV1->5

LOAD LOCK
CHAMBER =<250
MICRONS
PIR1

OPEN
LOAD LOCK
CHAMBER
VENT VALVE
CV1
BLOWER 1
ENABLED
BL1
DOOR 1
CLOSED
DRCL1S
1:006



MECHANICAL OPEN
PUMP 1 LOAD LOCK



O:010/11 - | | - File #2 MAIH_PRGRM - 168
 File #5 FAULTS - 159
 File #6 TECH_RUNGS - 0
 -|/| - File #5 FAULTS - 161
 -() - File #2 MAIH_PRGRM - 167

Rung #168

| OPEN
 | AUTO LOAD LOCK
 | MODE ROUGH
 | ENABLE VALVE
 | AUTO RV1

| N7:37 O:010
 | 11 11
 | [158] [167]

LOAD LOCK
 ROUGH TIMER
 LLRUFFTMR

TON	
TIMER ON DELAY	(EN)
TIMER: T4:113	
BASE (SEC): 1.0	(DN)
PRESET: 60	
ACCUM: 0	

T4:113.DN - | | - File #2 MAIH_PRGRM - 169

Rung #169

| LLRUFFTMR
 | T4:113

| DN
 | [168]

LOAD LOCK
 ROUGHING
 >60 SECONDS
 LLRUF>60
 83
 (L)
 816

83/816 - | | - File #2 MAIH_PRGRM - 626
 -(L)- - File #2 MAIH_PRGRM - 169
 -(U)- - File #2 MAIH_PRGRM - 170

Rung #170

| PAUSE
 | DISABLE
 | TS12
 | N7:16

| 4
 | [3]

LOAD LOCK
 ROUGHING
 >60 SECONDS
 LLRUF>60
 83
 (U)
 816

83/816 - | | - File #2 MAIH_PRGRM - 626
 -(L)- - File #2 MAIH_PRGRM - 169
 -(U)- - File #2 MAIH_PRGRM - 170

218

Rung #171

HEATER 1
CHAMBER
VENT 1 GATE VALVE
STAGE 1 CLOSE
V1ST1 HVIS1
83 1:002

412 06
[409]

T4:1.DN - - - File #2 MAIN_PRGRM - 173

DOOR 1
CLOSED
DRCL1S
1:006

00

VENT 1 STAGE1
DELAY TIMER
VIDYTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:1
BASE (SEC): 1.0 (DN)
PRESET: 5
ACQUM: 0

Rung #172

DOOR 2
CLOSED
DRCL2S
1:006

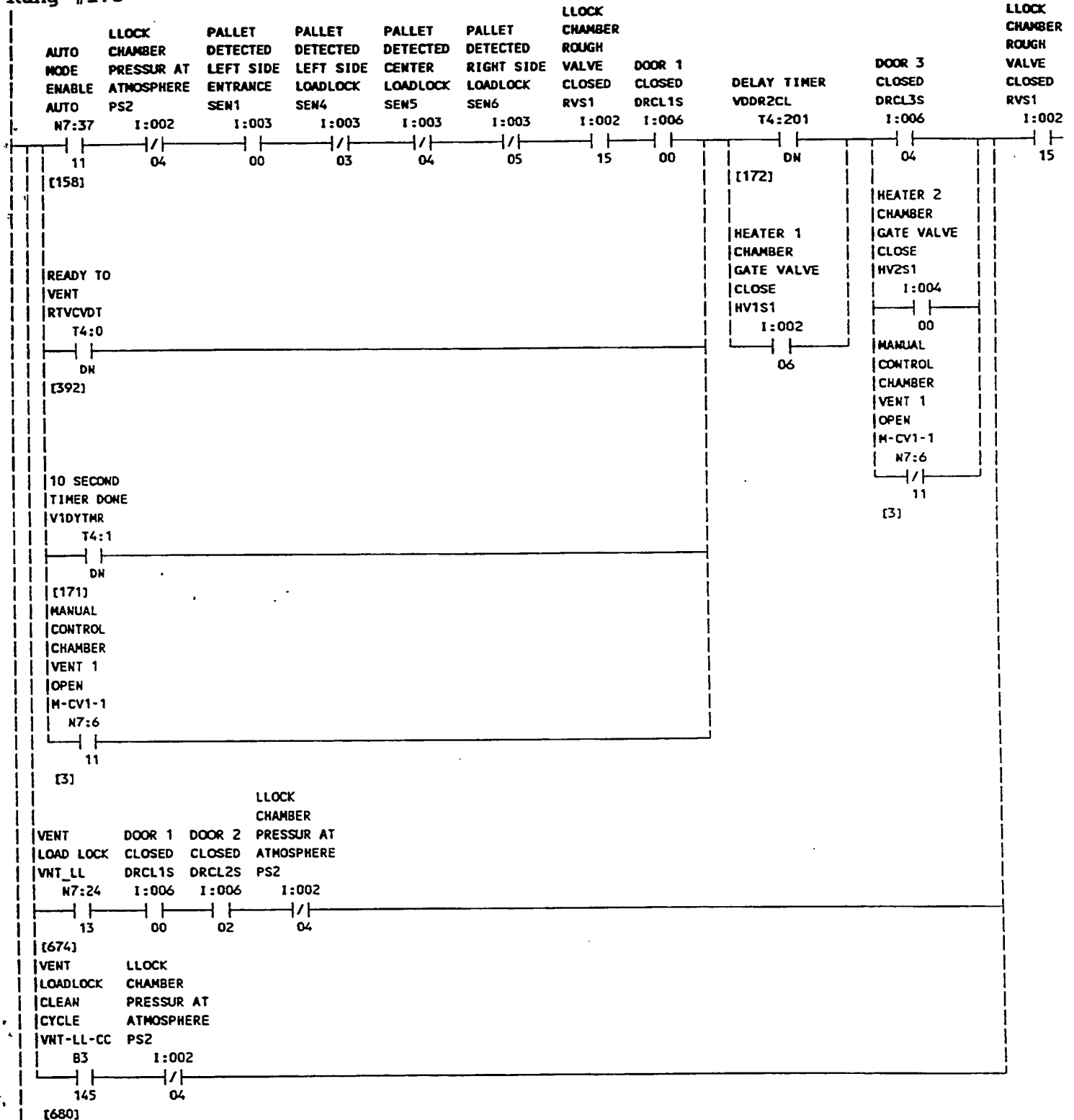
02

T4:201.DN - - - File #2 MAIN_PRGRM - 173

VENT DELAY
ON DOOR 2
CLOSE.
VDDR2CL

TON
TIMER ON DELAY (EN)
TIMER: T4:201
BASE (SEC): 1.0 (DN)
PRESET: 2
ACQUM: 0

Rung #173



OPEN
LOAD LOCK

CHAMBER
VENT VALVE
CV1
0:007
—(L)—
16

0:007/16 - | | - File #2 MAIH_PRGRM - 174
File #6 TECH_RUNGS - 0
-|/| - File #2 MAIH_PRGRM - 67,167,181,181,368,436,675,681
-(L)- - File #2 MAIH_PRGRM - 173
-(U)- - File #2 MAIH_PRGRM - 177

Rung #174

OPEN
|AUTO LOAD LOCK
|MODE CHAMBER
|ENABLE VENT VALVE
|AUTO CV1

ENTRANCE
LOCK VENT
TIMER
LDVNTTIMER

N7:37 0:007
| |
11 16
[158] [173]

TON
TIMER ON DELAY (EN)
TIMER: T4:143
BASE (SEC): 1.0 (DN)
PRESET: 100
ACCUM: 0

T4:143.DN - | | - File #2 MAIH_PRGRM - 175

Rung #175

LDVNTTIMER
T4:143

LOAD LOCK
VENT >30 SECS
LLVNT>30SECS

DN
[174]

B3
(L)
814

83/814 - | | - File #2 MAIH_PRGRM - 626
-(L)- - File #2 MAIH_PRGRM - 175
-(U)- - File #2 MAIH_PRGRM - 176

Rung #176

PAUSE
|DISABLE
|TS12
N7:16

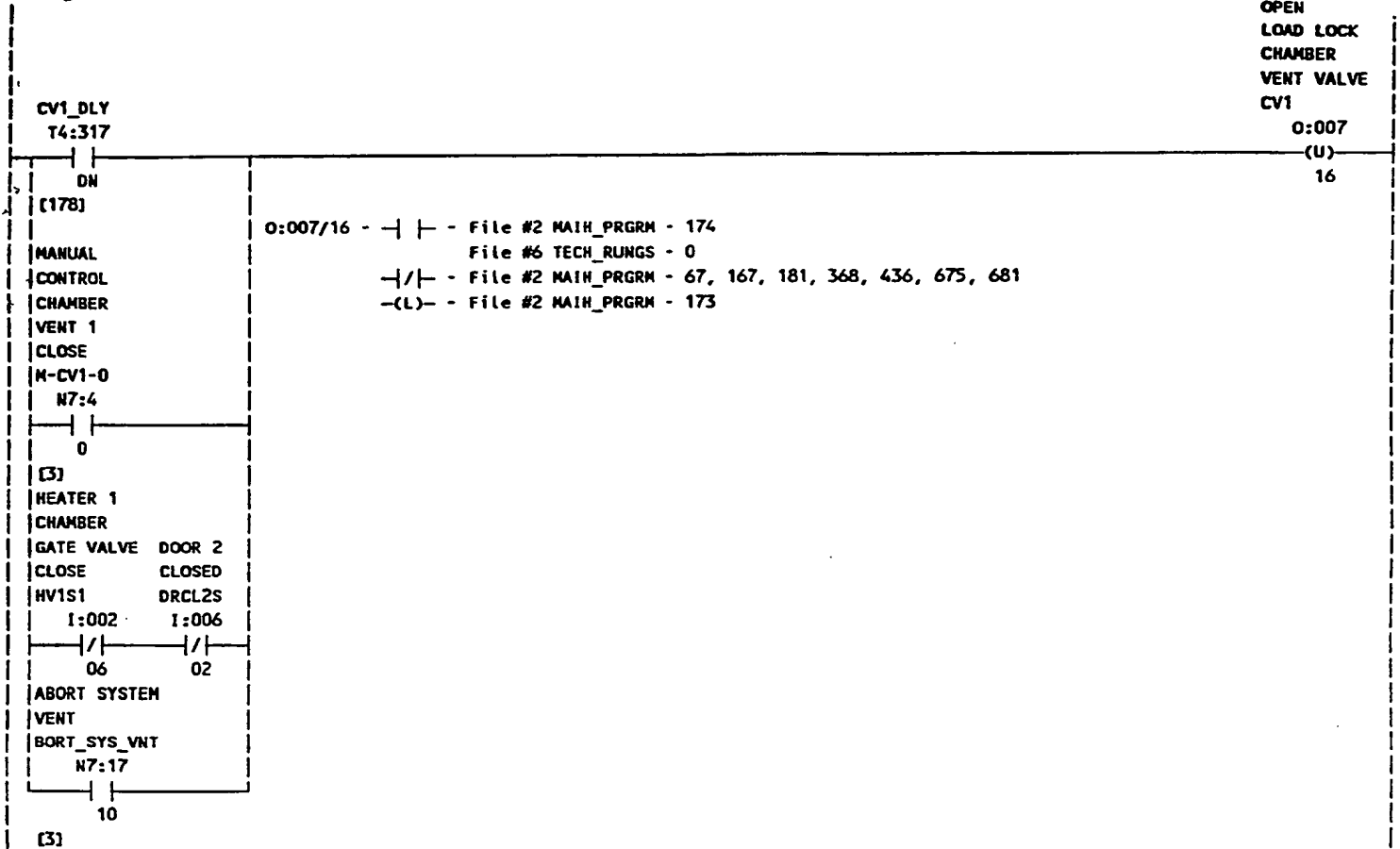
LOAD LOCK
VENT >30 SECS
LLVNT>30SECS

| |
4
[3]

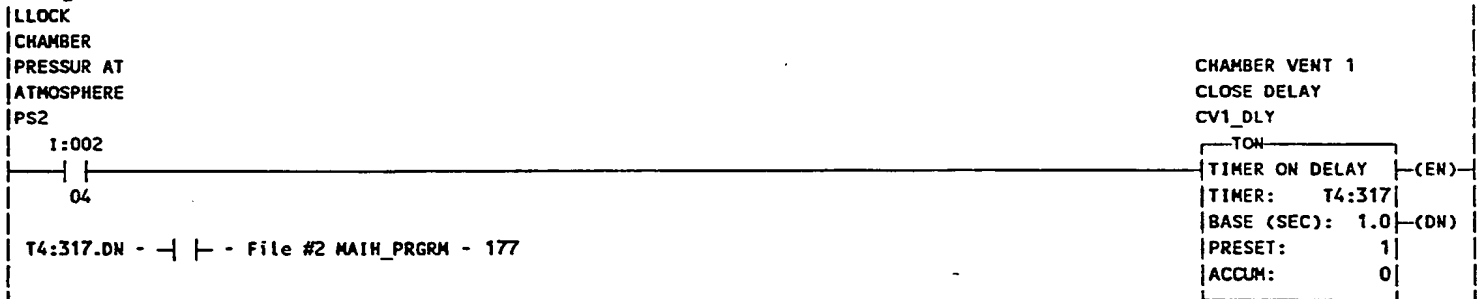
B3
(U)
814

83/814 - | | - File #2 MAIH_PRGRM - 626
-(L)- - File #2 MAIH_PRGRM - 175
-(U)- - File #2 MAIH_PRGRM - 176

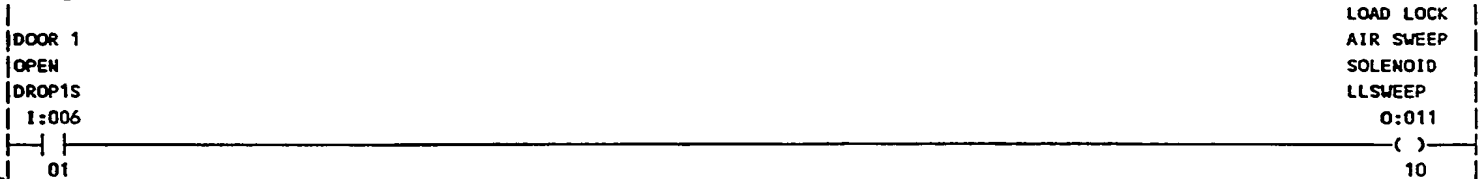
Rung #177



Rung #178



Rung #179



222

Rung #180

AUTO
MODE DOOR 1
ENABLE OPEN
AUTO DROP1S
N7:37 1:006

PALLET GATE

TIMER

PAL_GTE

TON

TIMER ON DELAY (EN)

TIMER: T4:77

BASE (SEC): 1.01 (DN)

PRESET: 115

ACCUM: 451

[158]

T4:77.TT - / - File #2 MAIN_PRGRM - 181

OPEN DOOR

1

DROP1

0:011

/

01

[181]

Rung #181

AUTO
MODE
ENABLE
AUTO
N7:37

PAL_GTE
T4:77

PALLET
DETECTED
RIGHT SIDE
ENTRANCE
SEN3

PALLET
DETECTED
CENTER
LOADLOCK
SEN5

OPEN
LOAD LOCK
CHAMBER
VENT VALVE
CV1

PAUSE
LATCH
ENABLE
PLE
N7:37

LLOCK
CHAMBER
PRESSUR AT
ATMOSPHERE
PS2

DOOR 1
OPEN
DROP1S
1:006

OPEN DOOR
1
DROP1
0:011

[158]

[180]

[177]

[025]

MANUAL
CONTROL

OPEN DOOR

MANUAL DOOR

1

1 OPEN

M-DROP-1

MDR1OP

N7:11

N7:32

7

(L)

[3]

PAL_GTE
T4:77

/

TT

[180]

PUMP-VENT
CYCLE LOAD
LOCK
PO-VMT-LL
N7:24

THREE CYCLES
COMPLETE
LL-CCC
C5:9

OPEN
LOAD LOCK
CHAMBER
VENT VALVE
CV1
0:007

[676]

[682]

[177]

MANUAL
CONTROL

OPEN DOOR

1

M-DROP-1

N7:11

7

[3]

0:011/01 - - - File #5 FAULTS - 41

File #6 TECH_RUNGS - 2

/ - - File #2 MAIN_PRGRM - 180

MANUAL DOOR

1 CLOSE

MDR1CL

N7:32

(U)

-()- - File #2 MAIN_PRGRM 181
 47:32/7 - -(L)- - File #2 MAIN_PRGRM - 181
 -(U)- - File #2 MAIN_PRGRM - 183
 F:W7:211121 - BTW - File #2 MAIN_PRGRM - 2
 47:31/11 - -(L)- - File #2 MAIN_PRGRM - 183
 -(U)- - File #2 MAIN_PRGRM - 181
 F:W7:211121 - BTW - File #2 MAIN_PRGRM - 2
 Rung #182

PALLET	PALLET	PALLET
DETECTED	DETECTED	DETECTED
CENTER	RIGHT SIDE	LEFT SIDE
ENTRANCE	ENTRANCE	LOADLOCK
SEN2	SEN3	SEN4
I:003	I:003	I:003

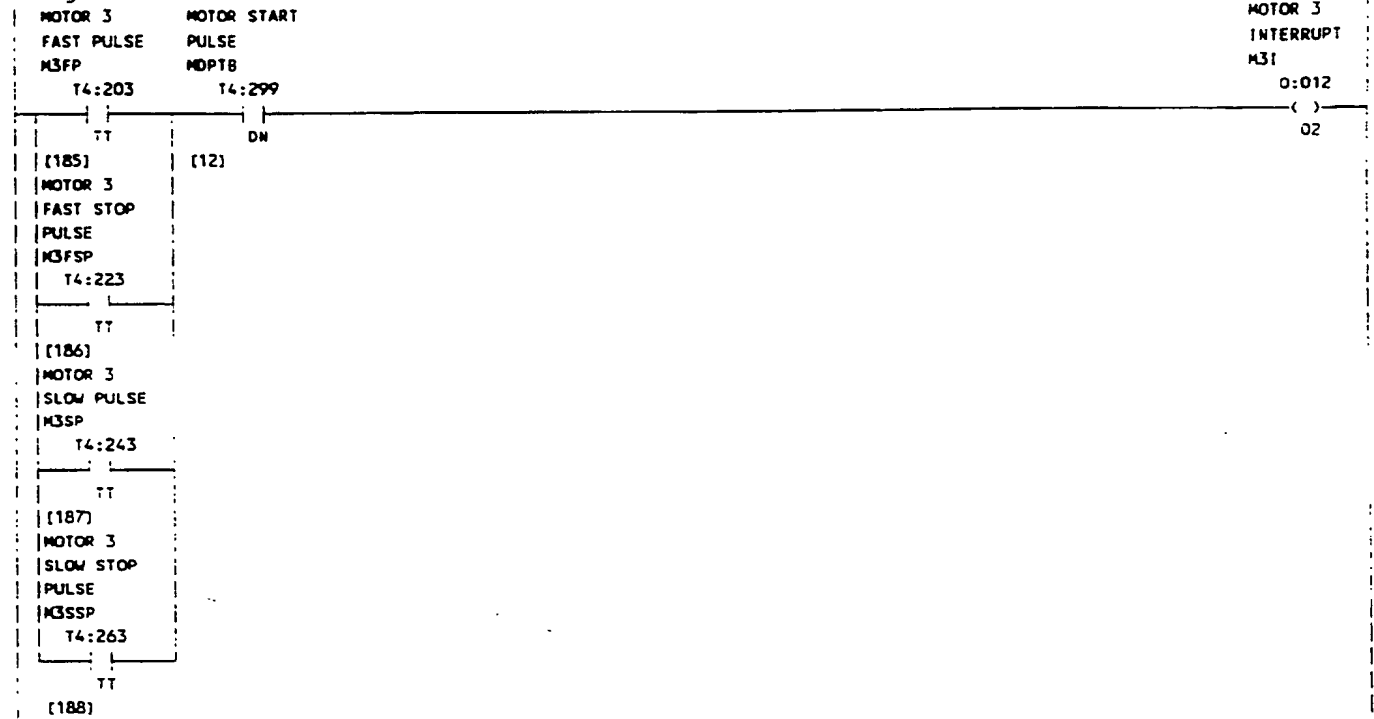
PALLET AT
 DOOR 1
 FLT_DR1
 S3
 198

01	02	03
PALLET	83/198 - -/ - File #2 MAIN_PRGRM - 183	
DETECTED		
CENTER		
LOADLOCK		
SEN5		
I:003		
04		

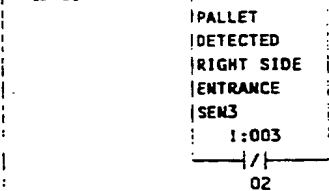
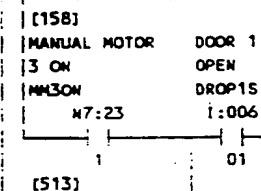
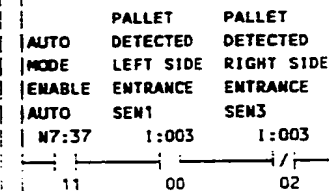
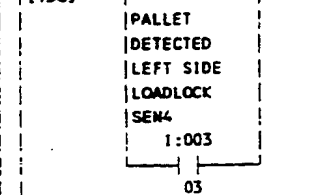
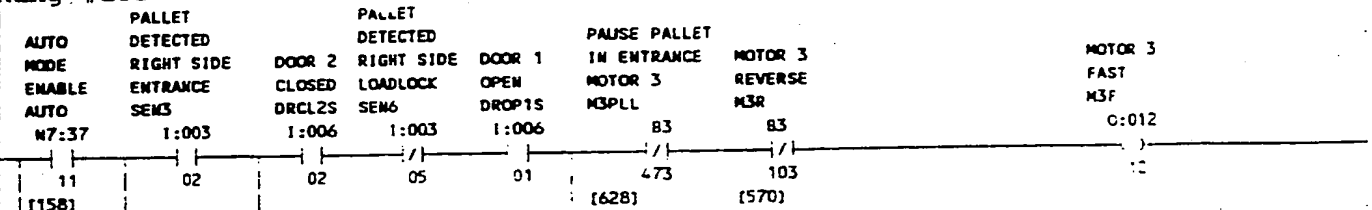
225

0:011/00 - File #5 FAULTS -
 File #6 TECH_RUNGS - 2
 () - File #2 MAIN_PRGRM - 183
 N7:32/7 - (L) - File #2 MAIN_PRGRM - 181
 (U) - File #2 MAIN_PRGRM - 183
 F:N7:211X21 - BTM - File #2 MAIN_PRGRM - 2
 N7:31/11 - (L) - File #2 MAIN_PRGRM - 183
 (U) - File #2 MAIN_PRGRM - 181
 F:N7:211X21 - BTM - File #2 MAIN_PRGRM - 2

Rung #184

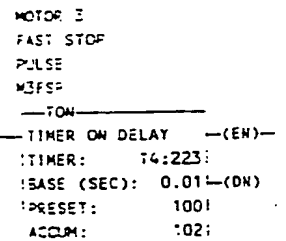
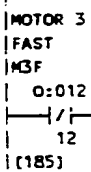


Rung #185



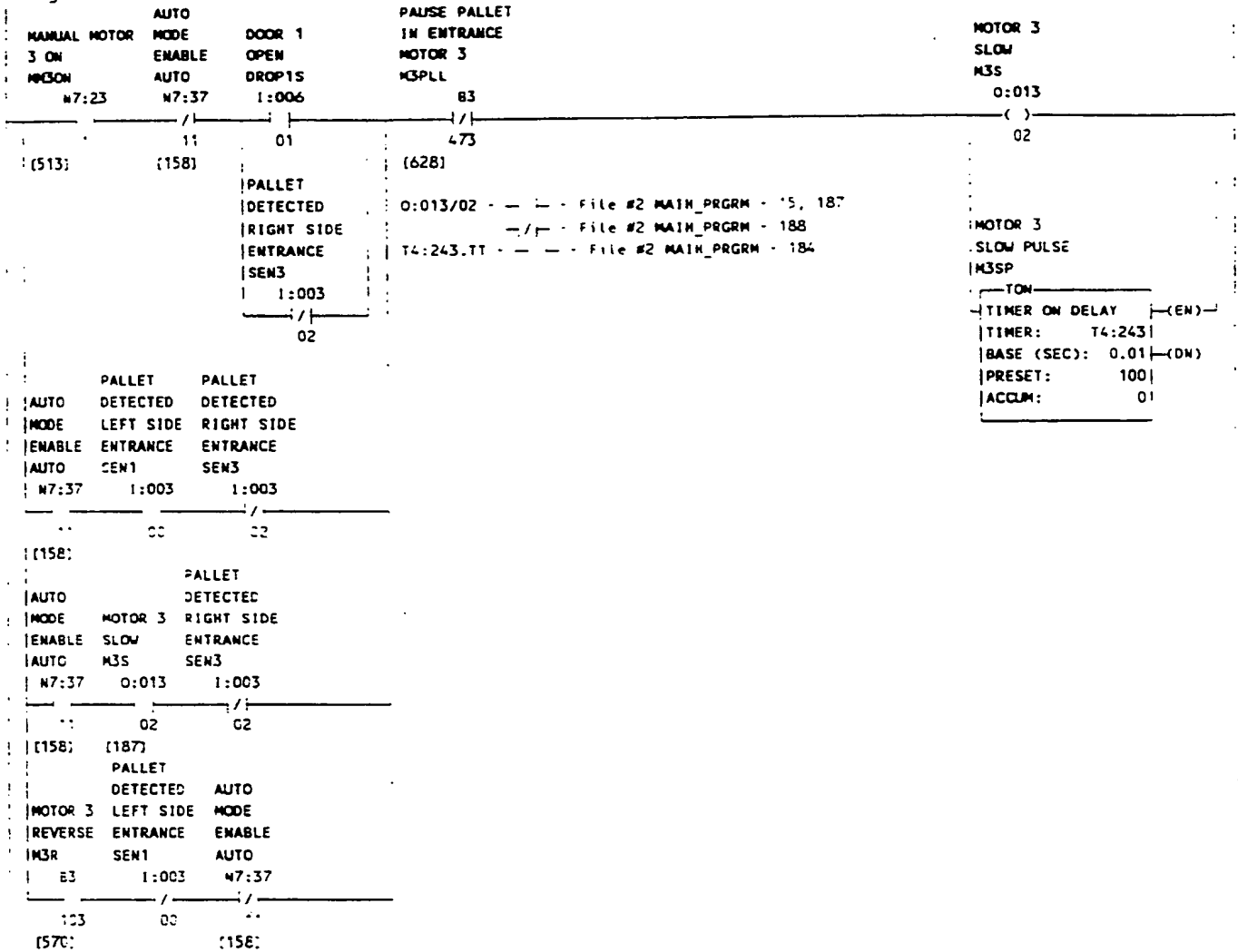
0:012/12 - File #5 FAULTS - 0
 - File #2 MAIN_PRGRM - 186
 - File #2 MAIN_PRGRM - 185
 74:203.TT - File #2 MAIN_PRGRM - 184

Rung #186

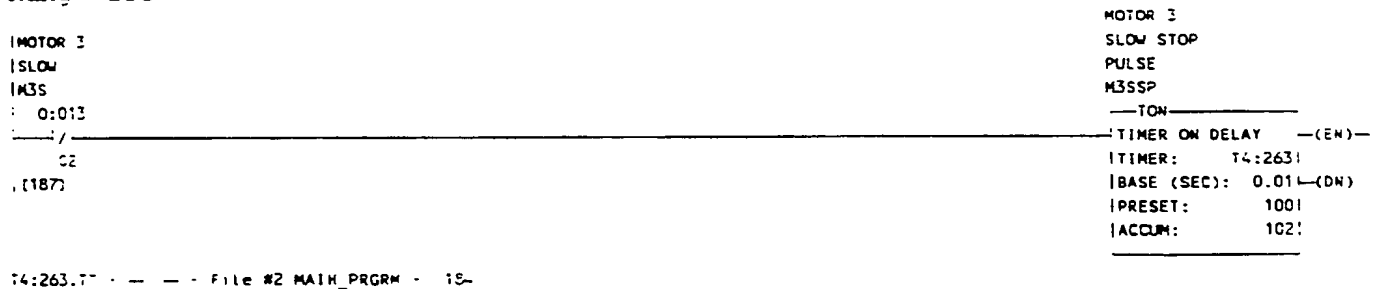


74:223.TT - File #2 MAIN_PRGRM - 184

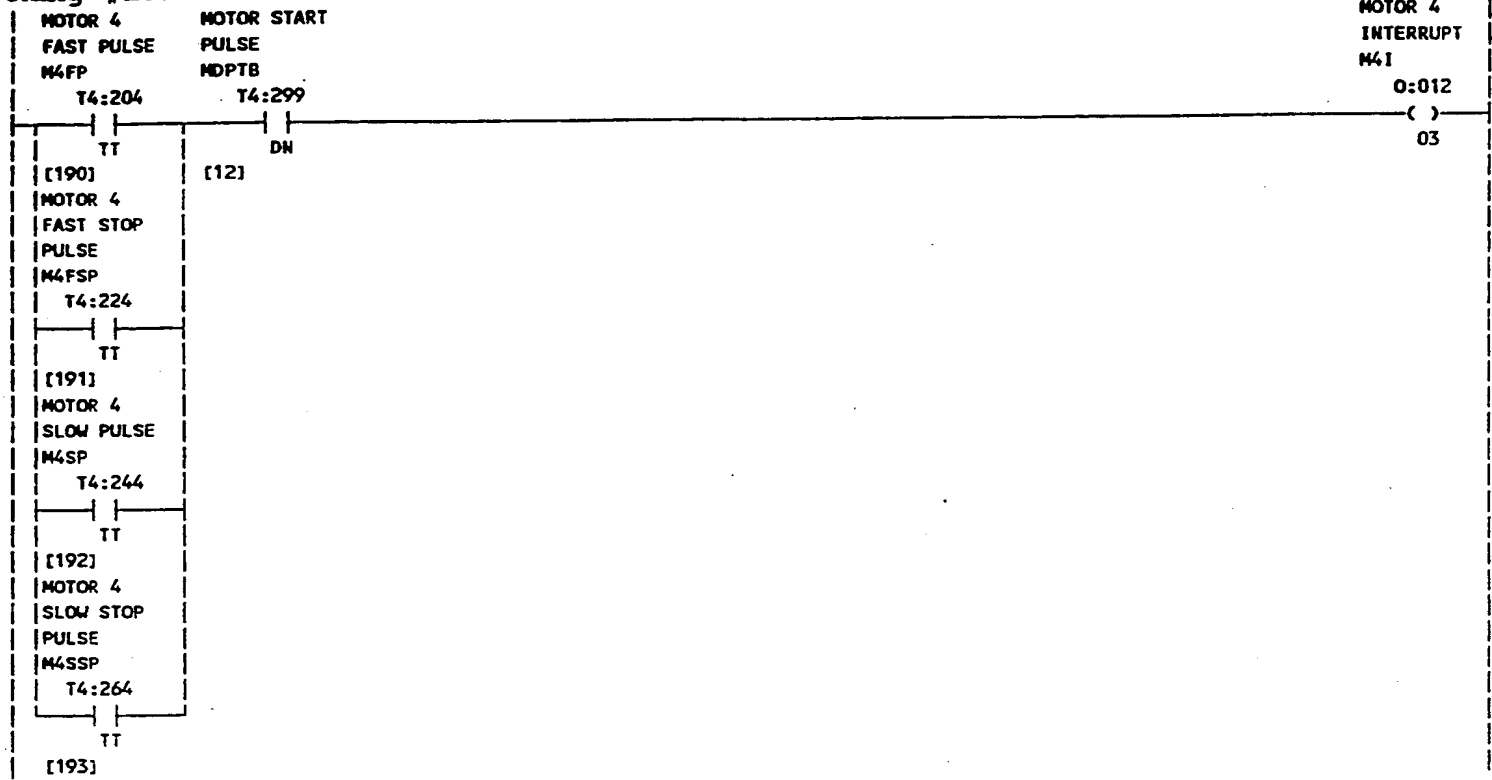
Rung #187



Rung #188



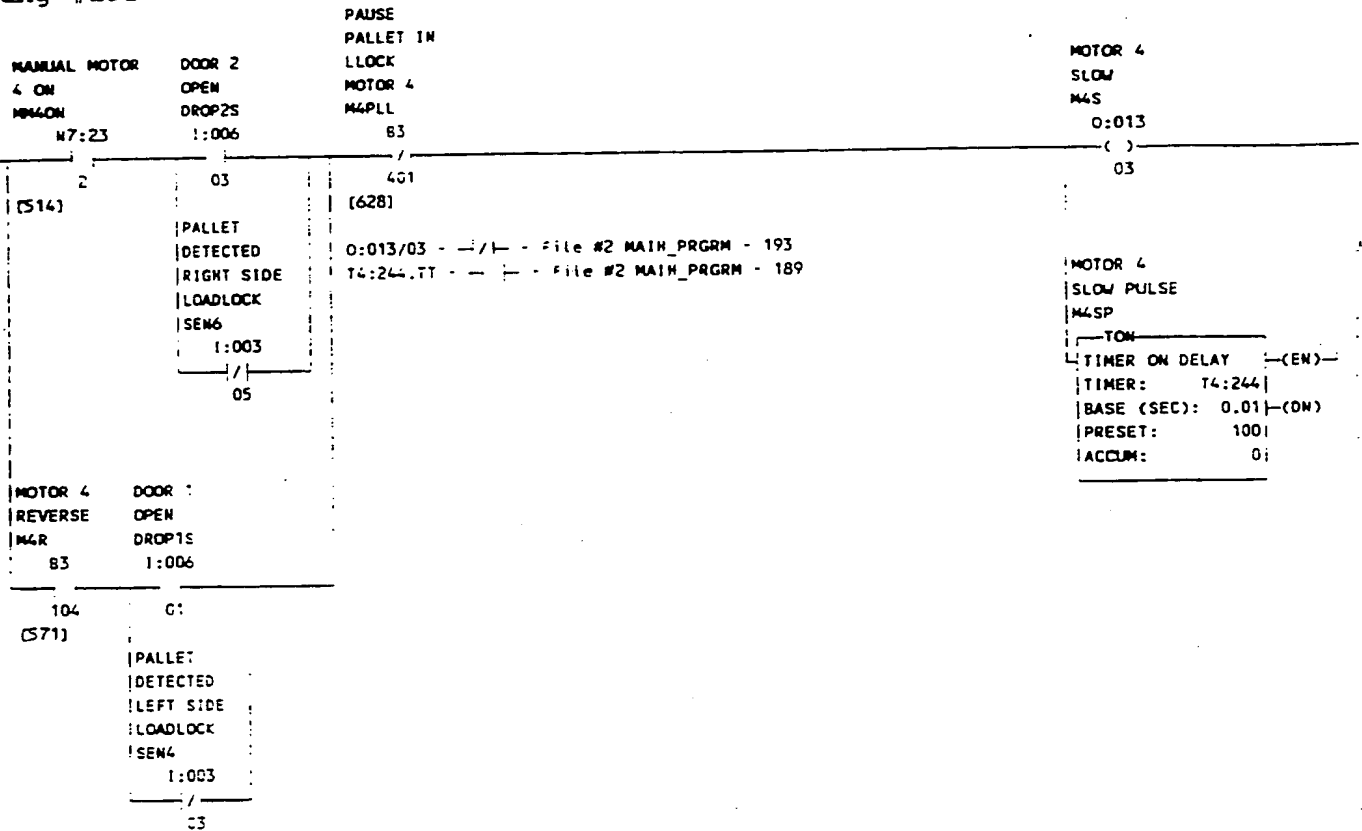
Rung #189



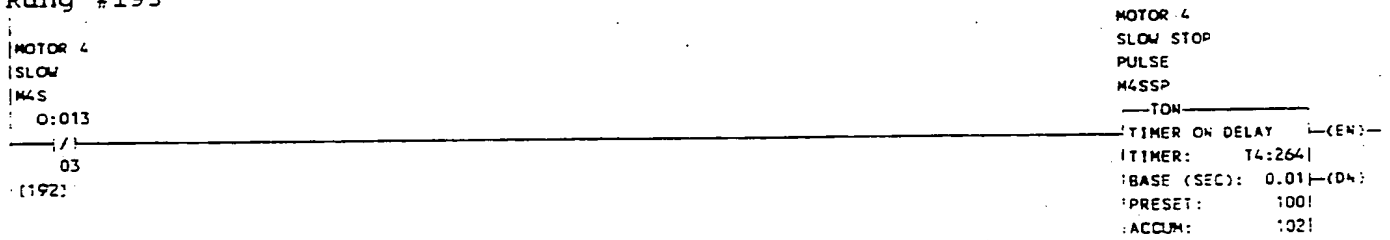


230

Rung #192



Rung #193



T4:264.TT - - - File #2 MAIN_PRGRM - 189

231

Rung #194

MOTOR 5
FAST PULSE
MSFP
T4:205

MOTOR START
PULSE
MDPTB
T4:299

MOTOR 5
INTERRUPT
MSI
O:012
()
04

TT
[195] [12]

MOTOR 5
FAST STOP
PULSE
MSFSP
T4:225

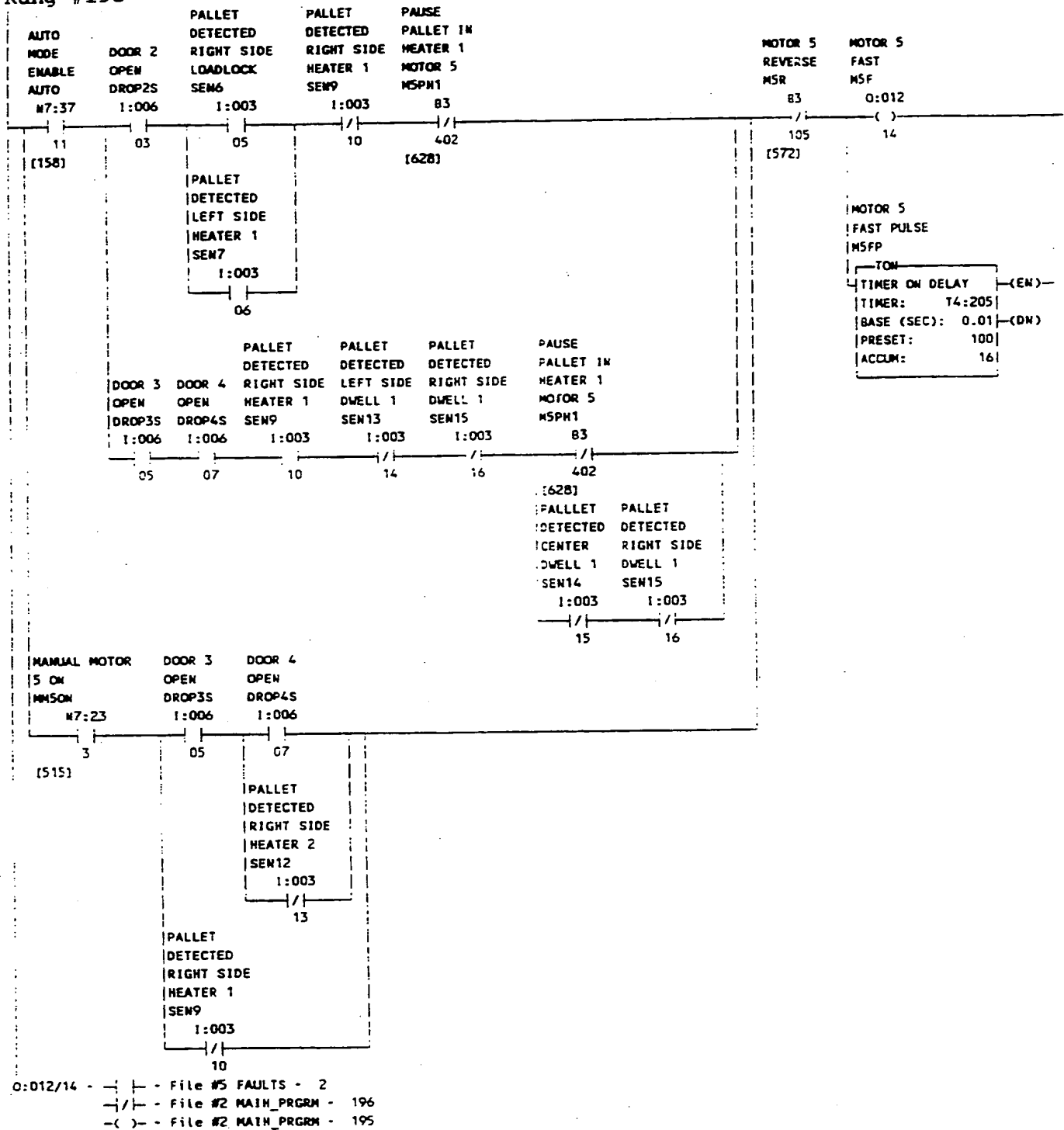
TT
[196]
MOTOR 5
SLOW PULSE
MSSP
T4:245

TT
[197]
MOTOR 5
SLOW STOP
PULSE
MSSSP
T4:265

TT
[198]

232

Rung #195



233

T4:205.TT - - - File #2 MAIN_PRGR - 194

Rung #196

MOTOR 5
FAST
PULSE
MSF

0:012

14

[195]

MOTOR 5
FAST STOP
PULSE
MSFSP

TON

TIMER ON DELAY (EN)

TIMER: T4:225

BASE (SEC): 0.01 (DN)

PRESET: 100

ACCUM: 0

T4:225.TT - - - File #2 MAIN_PRGR - 194

Rung #197

AUTO	DOOR 3	DOOR 4	PALLET DETECTED RIGHT SIDE	PALLET DETECTED LEFT SIDE	PALLET DETECTED RIGHT SIDE	PAUSE PALLET IN HEATER 1
MODE	OPEN	OPEN	HEATER 1	DWELL 1	DWELL 1	MOTOR 5
ENABLE	DROP3S	DROP4S	SEN9	SEN13	SEN15	MSPH1
AUTO	1:006	1:006	1:003	1:003	1:003	63

MOTOR 5
SLOW
MSS

0:013

1	05	07	10	14	16	402	04
[158]						[628]	

MANUAL MOTOR	DOOR 3	DOOR 4
IS ON	OPEN	OPEN
MMSON	DROP3S	DROP4S
47:23	1:006	1:006

PALLET DETECTED CENTER	PALLET DETECTED RIGHT SIDE
DWELL 1	DWELL 1
SEN14	SEN15
1:003	1:003

MOTOR 5
SLOW PULSE
MSSP

TON

TIMER ON DELAY (EN)

TIMER: T4:245

BASE (SEC): 0.01 (DN)

PRESET: 100

ACCUM: 0

1	05	07	10	14	16
[515]					

PALLET DETECTED RIGHT SIDE HEATER 2 SEN12 1:003 13
--

PALLE DETECTED RIGHT SIDE HEATER 1 SEN9 1:003 10
--

MOTOR 5	DOOR 2
REVERSE	OPEN
MSR	DROP2S
63	1:006

105	03
(572)	

PALLE DETECTED LEFT SIDE HEATER 1 SEN7 1:003

234

06
 0:013/04 - | | - File #2 MAIN_PRGRM - 198
 - () - File #2 MAIN_PRGRM - 197
 T4:265.TT - | | - File #2 MAIN_PRGRM - 194
 Rung #198

MOTOR 5
 SLOW
 MSS

0:013
 | |
 04
 [197]

MOTOR 5
 SLOW STOP
 PULSE
 MSSSP

TON
 TIMER ON DELAY --(EN)--
 TIMER: T4:265|
 BASE (SEC): 0.01--(DN)
 PRESET: 100|
 ACCUM: 102|

T4:265.TT - | | - File #2 MAIN_PRGRM - 194
 Rung #199

LLOCK
 CHAMBER
 ROUGH AUTO
 VALVE MODE
 CLOSED ENABLE
 RVS1 AUTO

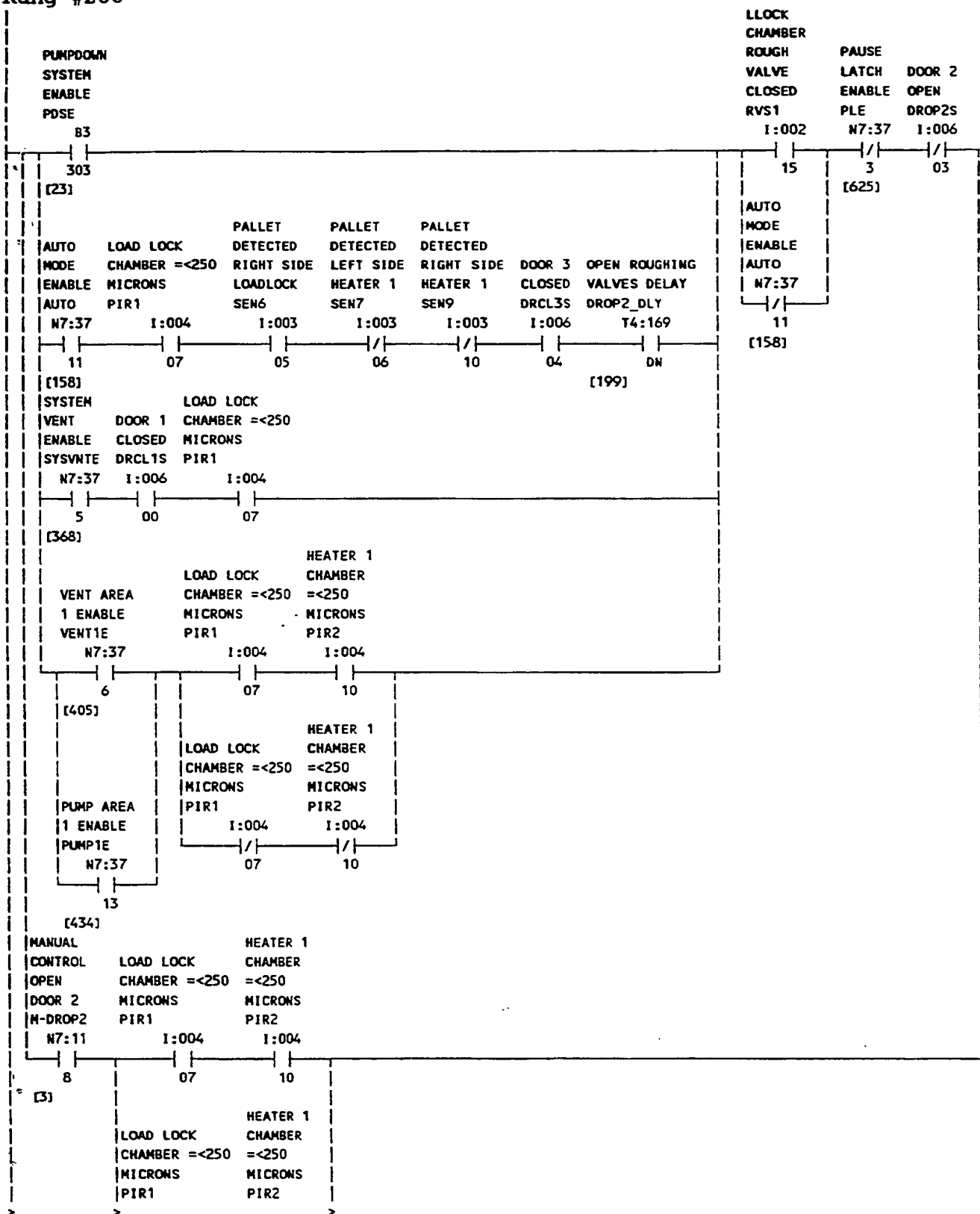
1:002 W7:37
 15 11
 [158]

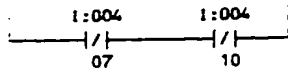
DOOR 2 OPEN
 DELAY
 CROP2_CLT

TON
 TIMER ON DELAY --(EN)--
 TIMER: T4:169|
 BASE (SEC): 1.0--(DN)
 PRESET: 2
 ACCUM: 2

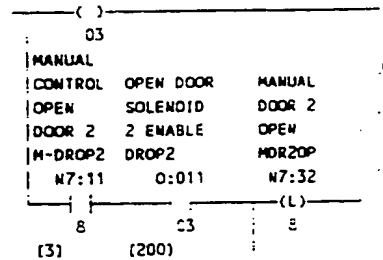
T4:169.DM - | | - File #2 MAIN_PRGRM - 104,200

Rung #200





OPEN DOOR
SOLENOID
2 ENABLE
DROP2
O:011



MANUAL
DOOR 2
CLOSE
MDR2CL
N7:31
()
12

O:011/03 - - - File #2 MAIN_PRGRM - 200
File #5 FAULTS - 43
File #6 TECH_RUNGS - 2
-()- - File #2 MAIN_PRGRM - 200
N7:32/8 - -(L)- - File #2 MAIN_PRGRM - 200
-(U)- - File #2 MAIN_PRGRM - 202
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:31/12 - -(L)- - File #2 MAIN_PRGRM - 202
-(U)- - File #2 MAIN_PRGRM - 200
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
Rung #201

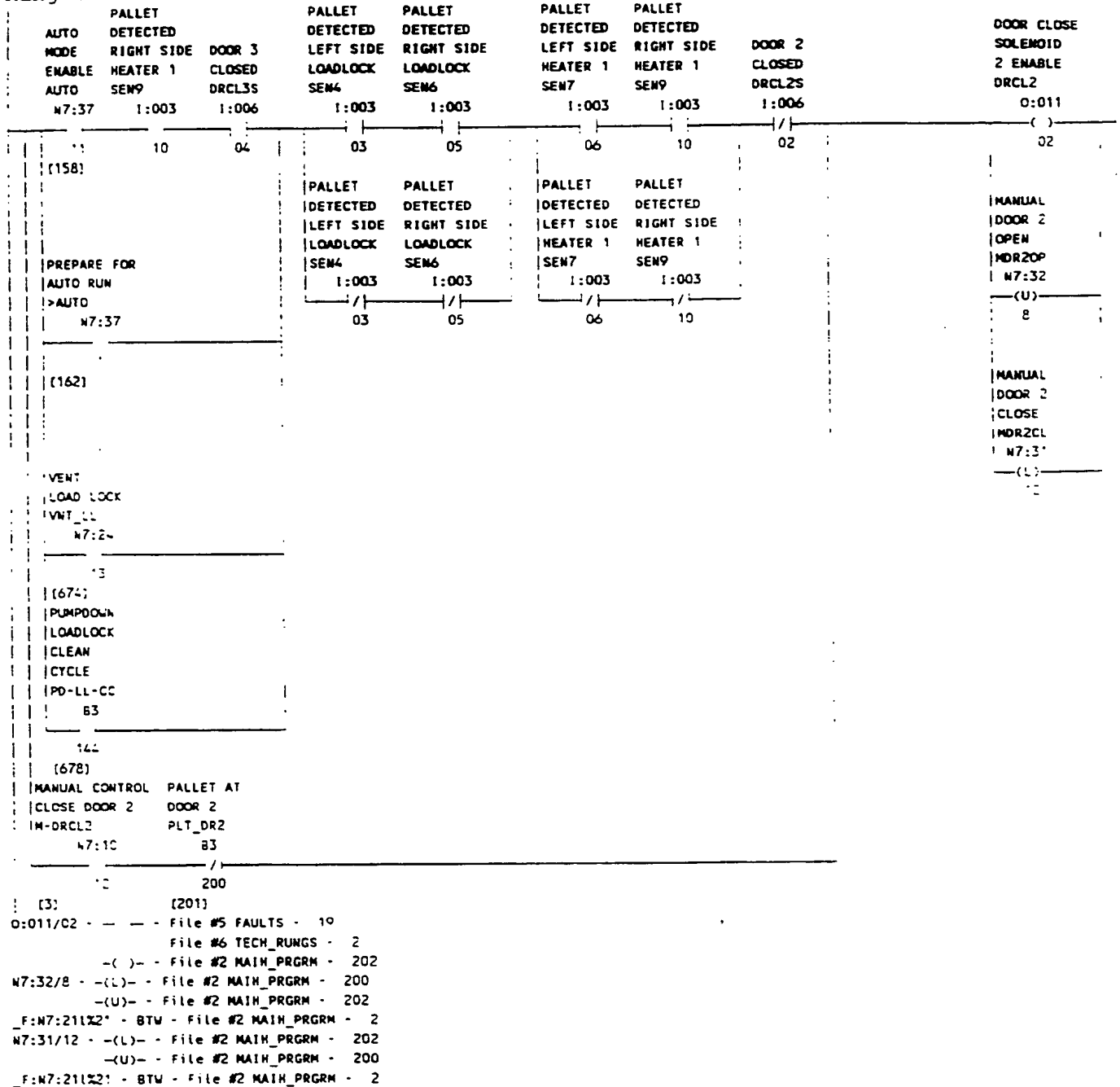
PALLET PALLET PALLET
DETECTED DETECTED DETECTED
CENTER RIGHT SIDE LEFT SIDE
LOADLOCK LOADLOCK HEATER 1
SENS5 SENS6 SENS7
1:003 1:003 1:003

PALLET AT
DOOR 2
PLT_DR2
S3

04 05 06
B3/200 - - / - - File #2 MAIN_PRGRM - 202
-()- - File #2 MAIN_PRGRM - 201

237

Rung #202



238

Rung #203

DOOR OPEN
SOLENOID
3 ENABLE
DROP3

0:011
05
[216]

TEST COUNTER
TST_CNTR

CTU
COUNT UP (CU)
COUNTER: CS:0
PRESET: (DN)
ACCUM: 98

CS:0 - CTU - File #2 MAIN_PRGRM - 203
RES - File #2 MAIN_PRGRM - 212

Rung #204

PALLET
AUTO DETECTED
MODE RIGHT SIDE
ENABLE HEATER 1
AUTO SEN9

N7:37 1:003
11 10
[158]

SENSOR 9
LATCH
SEN9_LTCH
83
(L)
329

83/329 - File #2 MAIN_PRGRM - 206
-(L)- File #2 MAIN_PRGRM - 204
-(U)- File #2 MAIN_PRGRM - 205

Rung #205

PALLET PALLET
AUTO DETECTED DETECTED
MODE RIGHT SIDE LEFT SIDE
ENABLE HEATER 2 DWELL 1
AUTO SEN12 SEN13

N7:37 1:003 1:003
11 13 14
[158]

SENSOR 9
LATCH
SEN9_LTCH
83
(U)
329

83/329 - File #2 MAIN_PRGRM - 206
-(L)- File #2 MAIN_PRGRM - 204
-(U)- File #2 MAIN_PRGRM - 205

Rung #206

AUTO
MODE SENSOR 9
ENABLE LATCH
AUTO SEN9_LTCH

N7:37 83
11 329
[158] [205]

CHART RECORDER
COUNTER 1
CHRTCNTR1

CTU
COUNT UP (CU)
COUNTER: CS:29
PRESET: (DN)
ACCUM: 98

CS:29 - CTU - File #2 MAIN_PRGRM - 206
RES - File #2 MAIN_PRGRM - 212

CS:29.ACC - NEQ - File #2 MAIN_PRGRM - 210

Rung #207

PALLET PALLET
AUTO DETECTED DETECTED
MODE CENTER RIGHT SIDE
ENABLE CARBON CARBON
AUTO SEN41 SEN42

N7:37 1:053 1:053
11 01 02
[158]

SENSOR 42
LATCH
SEN42_LTCH
83
(L)
330

63/330 - - - File #2 MAIN_PRGRM - .09
 -(L)- - File #2 MAIN_PRGRM - 207
 -(U)- - File #2 MAIN_PRGRM - 208

Rung #208

| PALLET PALLET
 | AUTO DETECTED DETECTED
 | MODE CENTER RIGHT SIDE
 | ENABLE DWELL 6 DWELL 6
 | AUTO SEN44 SEN45
 | M7:37 1:053 1:053

SENSOR 42
 LATCH
 SEN42_LTCH
 83

11 04 05 (U) 330

(158)
 63/330 - - - File #2 MAIN_PRGRM - 209
 -(L)- - File #2 MAIN_PRGRM - 207
 -(U)- - File #2 MAIN_PRGRM - 208

Rung #209

| AUTO
 | MODE SENSOR 42
 | ENABLE LATCH
 | AUTO SEN42_LTCH
 | M7:37 83

CHART RECORDER
 COUNTER 2
 CHRTCNTR2
 CTU
 COUNT UP (CU)
 COUNTER: CS:301
 PRESET: 9 (DN)
 ACCUM: 96

11 330 (158) (208)

CS:30 - CTU - File #2 MAIN_PRGRM - 209
 RES - File #2 MAIN_PRGRM - 212
 CS:30.ACC - NEG - File #2 MAIN_PRGRM - 210
 Rung #210

| CHRTCNTR1
 | -NEG
 | NOT EQUAL (A<>B)
 | SOURCE A: CS:29.ACC1
 | 98
 | SOURCE B: CS:30.ACC1
 | 96

CHART RECORDER
 1 ON
 CHRTCNTR1
 0:044
 ()
 00

CS:29.ACC - (212)
 CS:30.ACC - (209)

CHART RECORDER
 2 ON
 CHRTCNTR2
 0:044
 ()
 00

Rung #211

| AUTO PALLET
 | DETECTED
 | MODE DOOR 2 DOOR 3 RIGHT SIDE
 | ENABLE CLOSED CLOSED HEATER 1
 | AUTO DRCL2S DRCL3S SEN9
 | M7:37 1:006 1:006 1:003

HEATER1
 TIMEP
 TRITMR
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:74
 BASE (SEC): 1.0 (DN)
 PRESET: 60
 ACCUM: 0

11 02 04 10 (158)

T4:74.DN - - - File #2 MAIN_PRGRM - 214,226
 T4:74.DN - - - File #2 MAIN_PRGRM - 213

Rung #212

AUTO
MODE
ENABLE
AUTO
M7:37

TEST COUNTER
TST_CNTR
CS:0
(RES)

/|
11

[158]

CS:0 - CTU - File #2 MAIN_PRGRM - 203
CS:29 - CTU - File #2 MAIN_PRGRM - 206
CS:29.ACC - NEQ - File #2 MAIN_PRGRM - 210
CS:30 - CTU - File #2 MAIN_PRGRM - 209
CS:30.ACC - NEQ - File #2 MAIN_PRGRM - 210

CHART RECORDER
COUNTER 1
CHRTCNT1
CS:29
(RES)

CHART RECORDER
COUNTER 2
CHRTCNT2
CS:30
(RES)

Rung #213

HEATER
SHIELD H2C
FLOW
HEATER 1 GROUP 1
TIMER FAULT
HTR1TMR HSPG1F
T4:74 B3

SUBSTRATE
HEATER
SET HIGH
HH1A
0:046

/|
TT 216

(211) CS:190

0:046/00 - /| - File #2 MAIN_PRGRM - 153
0:046/01 - /| - File #2 MAIN_PRGRM - 153
0:046/05 - /| - File #2 MAIN_PRGRM - 153
0:046/06 - /| - File #2 MAIN_PRGRM - 153

()
00

SUBSTRATE
HEATER
SET HIGH
HH1B
0:046

()
01

SUBSTRATE
HEATER
SET HIGH
HH3A

0:046
()

05

SUBSTRATE
HEATER
SET HIGH
HH3B
0:046

()
06

241

Rung #214

AUTO	HEATER 1	PALLET DETECTED
MODE	COMPLETE	RIGHT SIDE
ENABLE	HTR1TMR	DWELL 1
AUTO	SEN15	
M7:37	T4:74	1:003
11	DN	16
(158)	(211)	

HEATER
DELAY
TIMER
HTRDLYTMR
TON
TIMER ON DELAY (EN)
TIMER: T4:75
BASE (SEC): 1.0 (DN)
PRESET: 25
ACCUM: 0

T4:75.DN - - - File #2 MAIN_PRGRM - 215
Rung #215

HTRDLYTMR
T4:75
DN
(214)
0:011/12 - - - File #2 MAIN_PRGRM - 379
- / - File #2 MAIN_PRGRM - 38
-(U)- File #2 MAIN_PRGRM - 116
T4:40.DN - - - File #2 MAIN_PRGRM - 216

HEATER 1
HIVAC BAFFLE
HV1_2
0:011
(L)
12

PAUSE	DOOR 3
LATCH	DELAY TIMER
ENABLE	DR30T
PLE	TON
M7:37	TIMER ON DELAY (EN)
/	TIMER: T4:40
3	BASE (SEC): 1.0 (DN)
(625)	PRESET: 5
	ACCUM: 0

PALLET	PALLET
DETECTED	DETECTED
CENTER	RIGHT SIDE
DWELL 1	DWELL 1
SEN14	SEN15
1:003	1:003
/	/
15	14

242

Rung #216

DOOR OPEN 3 DOOR 3
 DELAY OPEN
 DR30T DROP3S
 T4:40 1:006

DN 05

[215]

MANUAL HEATER 1 CHROME
 CONTROL CHAMBER CHAMBER
 OPEN DOOR =<250 =<250
 3 MICRONS MICRONS
 M-DROP3 PIR2 PIR6
 N7:11 1:004 1:024

9

10

07

[3]

PUMPDOWN
 SYSTEM
 ENABLE
 PDSE
 B3

303

[23]

SYSTEM
 VENT
 ENABLE
 SYSVTE
 N7:37

5

[368]

VENT AREA
 1 ENABLE
 VENT1E
 N7:37

6

[405]

PUMP AREA
 1 ENABLE
 PUMP1E
 N7:37

13

[434]

0:011/05 - | - File #2 MAIN_PRGRM - 203
 File #5 FAULTS - 45
 File #6 TECH_RUNGS - 2
 -() - File #2 MAIN_PRGRM - 216
 N7:32/9 - -(L)- File #2 MAIN_PRGRM - 216
 -(U)- File #2 MAIN_PRGRM - 229

DOOR OPEN
 SOLENOID
 3 ENABLE
 DROP3
 0:011

()

05

MANUAL DOOR OPEN MANUAL
 CONTROL OPEN DOOR 3
 3 3 ENABLE DOOR 3
 M-DROP3 DROP3 MDR3OP
 N7:11 0:011 N7:32

9

05

(L)

[3]

[216]

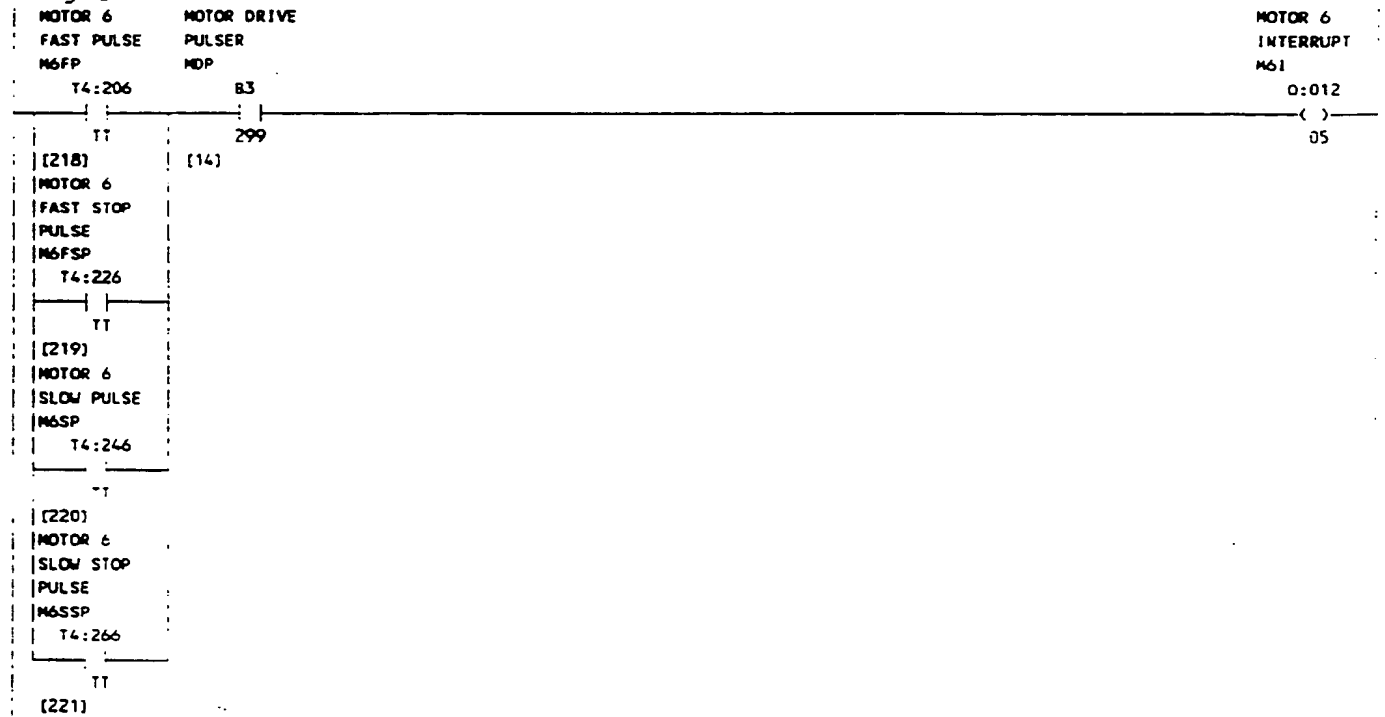
9

MANUAL
 DOOR 3
 CLOSE
 MDR3CL
 N7:31
 (U)
 13

243

F:M7:211X21 - BTW - File #2 MAIN_PRL - 2
N7:31/13 - (L) - File #2 MAIN_PRGRM - 229
(U) - File #2 MAIN_PRGRM - 216
F:M7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #217



Rung #219

MOTOR 6
FAST
M6F
O:012

|/|
15
[218]

MOTOR 6
FAST STOP
PULSE
M6FSP

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:226
BASE (SEC):	0.01 (DN)
PRESET:	100
ACCUM:	102

T4:226.TT - | | - File #2 MAIN_PRGRM - 217

Rung #220

MANUAL MOTOR DOOR 4
6 ON OPEN
MM6ON DROP4S
N7:23 I:006

|/|
4 07
[516]

PALLET
DETECTED
RIGHT SIDE
HEATER 2
SEN12
I:003
|/|
13

O:013/05 - |/| - File #2 MAIN_PRGRM - 221
T4:246.TT - | | - File #2 MAIN_PRGRM - 217

MOTOR 6
SLOW
M6S
O:013

()
05

MOTOR 6
SLOW PULSE
M6SP

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:246
BASE (SEC):	0.01 (DN)
PRESET:	100
ACCUM:	0

MOTOR 6 DOOR 3
REVERSE OPEN
M6R DROP3S
B3 I:006

|/|
106 05
[573]

PALLET
DETECTED
LEFT SIDE
HEATER 2
SEN10
I:003
|/|
11

Rung #221

MOTOR 6
SLOW
M6S
O:013

|/|
05
[220]

MOTOR 6
SLOW STOP
PULSE
M6SSP

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:266
BASE (SEC):	0.01 (DN)
PRESET:	100
ACCUM:	102

T4:266.TT - | | - File #2 MAIN_PRGRM - 217

246

Rung #222

AUTO PALLET
MODE DETECTED
LEFT SIDE
ENABLE DWELL 1
AUTO SEN13
N7:37 1:003

HEATER 2
DELAY OFF
TIMER
HTR2_OFF

11
[158]

14

PALLET
DETECTED
CENTER
DWELL 1
SEN14
1:003

T4:76.DN - - File #2 MAIN_PRGRM - 223

TOM
TIMER ON DELAY (EN)
TIMER: T4:76
BASE (SEC): 1.0 (DN)
PRESET: 13
ACCUM: 13

15

PALLET
DETECTED
RIGHT SIDE
DWELL 1
SEN15
1:003

16

Rung #223

HTR2_OFF
T4:76

HEATER 2
LATCH
HTR2LATCH
B3

DN

[222]

B3/320 - - File #2 MAIN_PRGRM - 225, 227
-(L)- - File #2 MAIN_PRGRM - 224

HSFFTR
T4:93

DN

(5:199)

AUTO OFF

PULSE

AUTOFFPULSE

T4:283

TT

[155]

PALLET

DETECTED

RIGHT SIDE HEATER LATCH

DWELL 1 UNLATCH

SEN15 HTR_UNLATCH

1:003 B3

(ONS)

16

411

Rung #224

HTR2ON_DY

T4:78

DN

[226]

B3/320 - | | - File #2 MAIN_PRGRM - 225,227

-(L)- File #2 MAIN_PRGRM - 224

-(U)- File #2 MAIN_PRGRM - 223

HEATER 2

LATCH

HTR2LTCH

B3

(L)

320

Rung #225

HEATER 2

LATCH

HTR2LTCH

B3

320

[224]

HEATER 2 DRIVE

FAULT TIMER

H2F

TON
TIMER ON DELAY
TIMER: T4:6
BASE (SEC): 1.0
PRESET: 70
ACCUM: 0

(EN)

(DN)

T4:6.DN - | | - File #2 MAIN_PRGRM - 227

Rung #226

AUTO

MODE HEATER 1 GROUP 2

ENABLE COMPLETE FAULT

AUTO HTR1TMR HSFG2F

W7:37 T4:74 B3

11 DN 217

[158] [211] [5:191]

heater 2 on

delay

HTR2ON_DY

TON
TIMER ON DELAY
TIMER: T4:78
BASE (SEC): 1.0
PRESET: 26
ACCUM: 0

(EN)

(DN)

T4:78.DN - | | - File #2 MAIN_PRGRM - 224

268

Rung #227

HEATER 2 HEATER 2 DRIVE
LATCH FAULT TIMER
HTR2LTCH H2F

SUBSTRATE
HEATER
SET HIGH
HH2A

O:046

()

02

83 T4:6
320 DM

[224] [225]

O:046/02 - | | - File #2 MAIN_PRGRM - 153
O:046/03 - | | - File #2 MAIN_PRGRM - 153
O:046/04 - | | - File #2 MAIN_PRGRM - 153
O:046/07 - | | - File #2 MAIN_PRGRM - 153

SUBSTRATE
HEATER
SET HIGH
HH2B

O:046

()

03

SUBSTRATE
HEATER
SET HIGH
HH2C

O:046

()

04

SUBSTRATE
HEATER
SET HIGH
HH3C

O:046

()

07

Rung #228

PALLET PALLET PALLET
DETECTED DETECTED DETECTED
CENTER RIGHT SIDE LEFT SIDE
HEATER 1 HEATER 1 HEATER 2
SEN8 SEN9 SEN10

PALLET AT
DOOR 3
PLT_DR3

1:003 1:003 1:003

()

83

246

07 10 11
PALLET B3/246 - | | - File #2 MAIN_PRGRM - 229

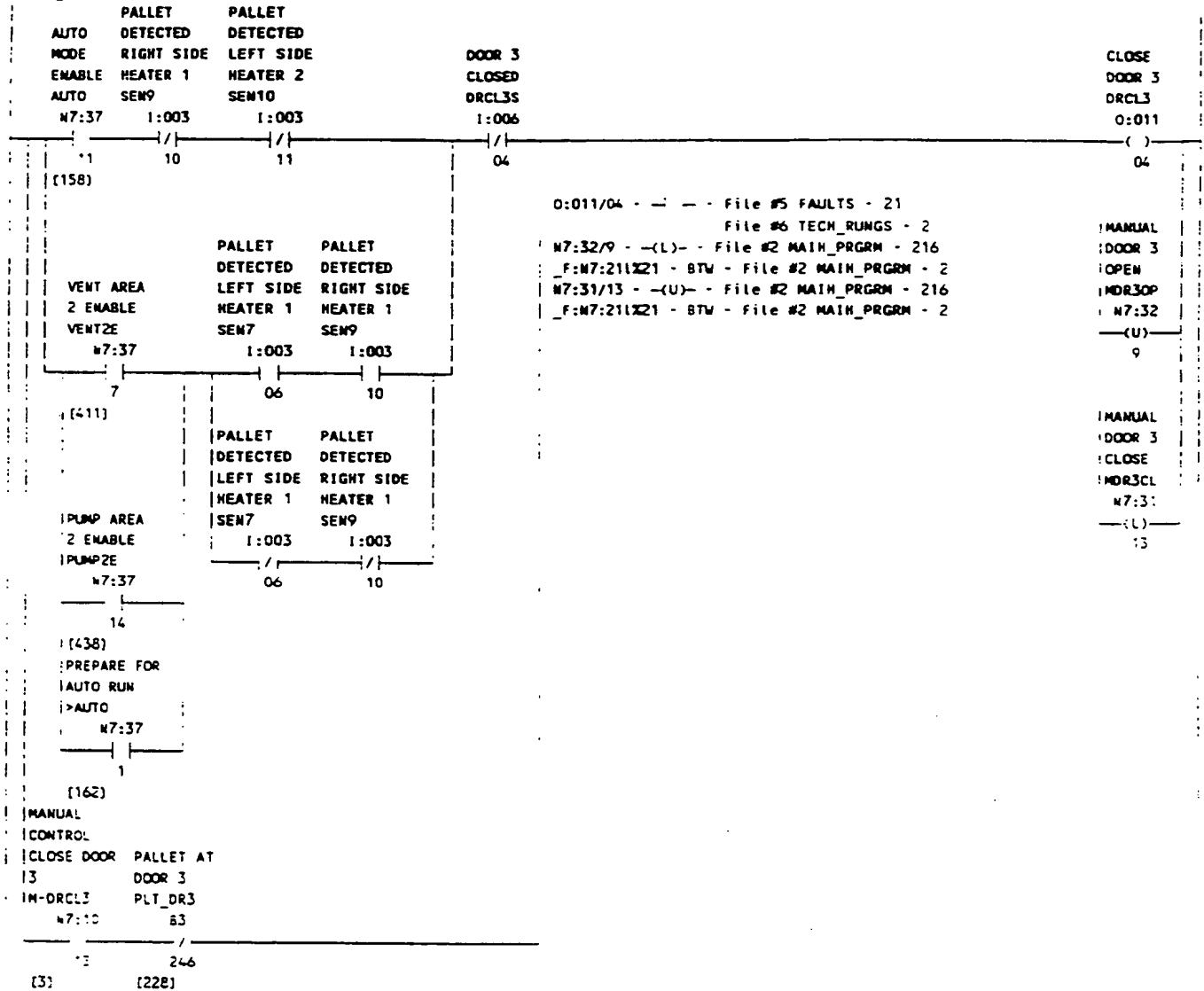
PALLET
DETECTED
RIGHT SIDE
HEATER 2
SEN12

1:003

13

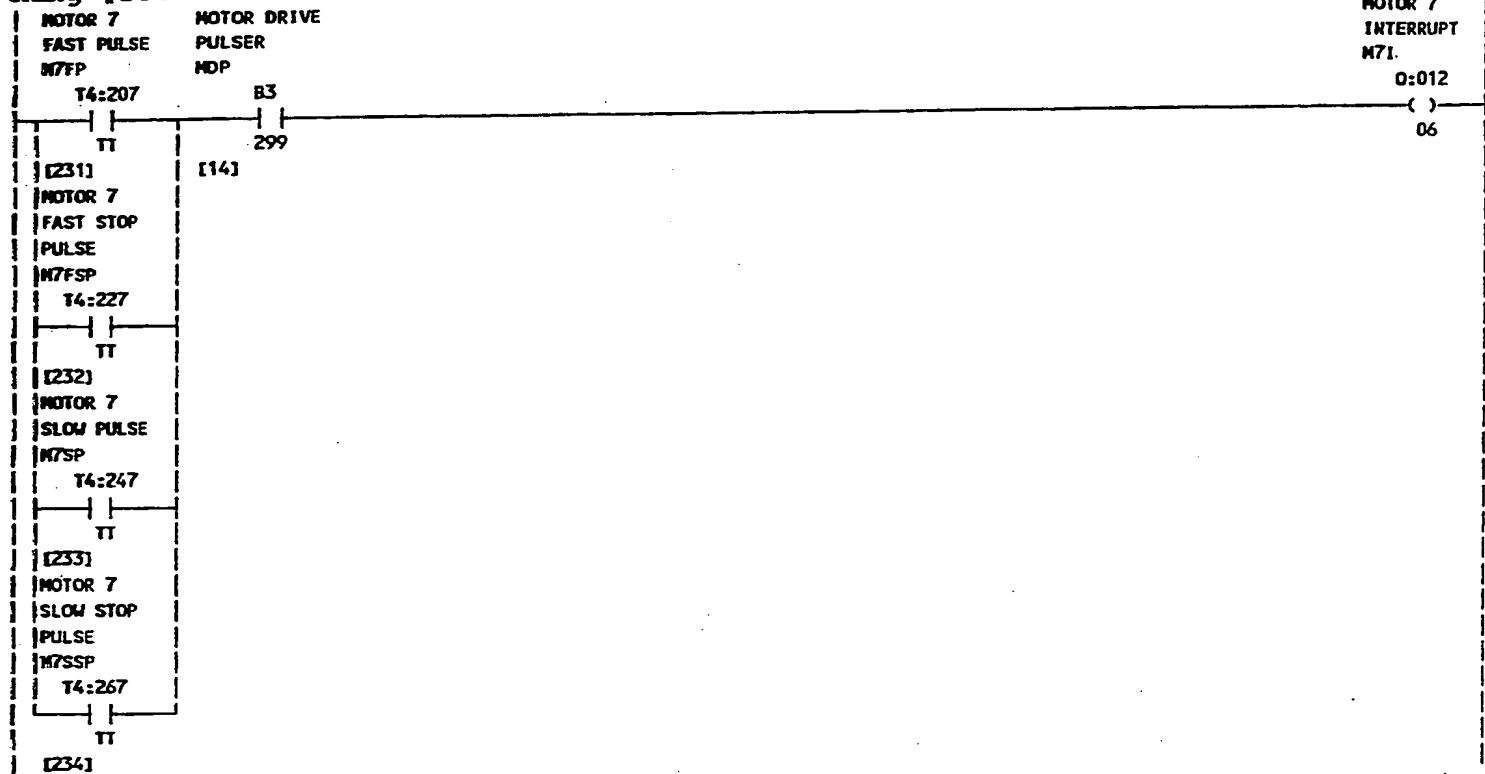
249

Rung #229



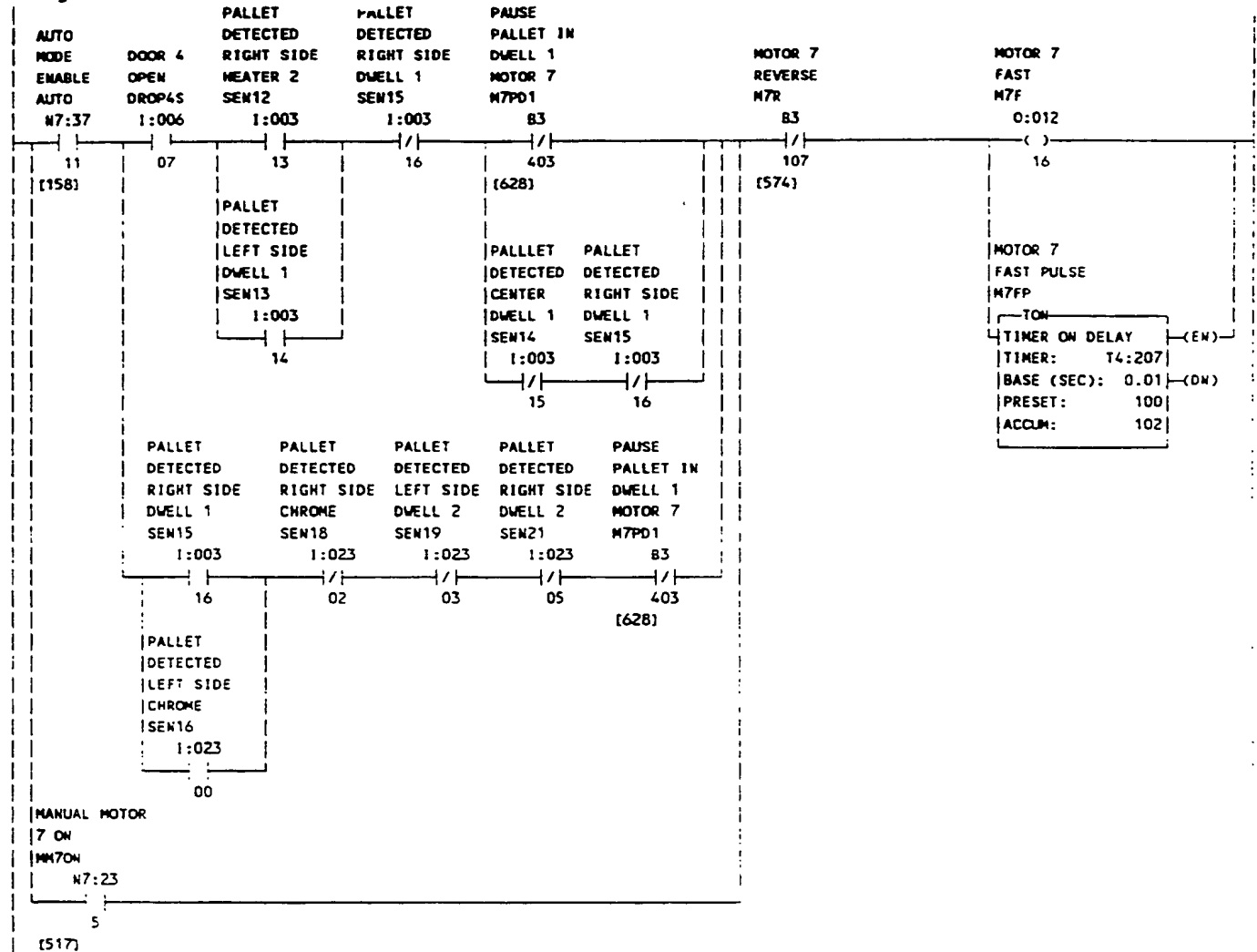
250

Rung #230



251

Rung #231



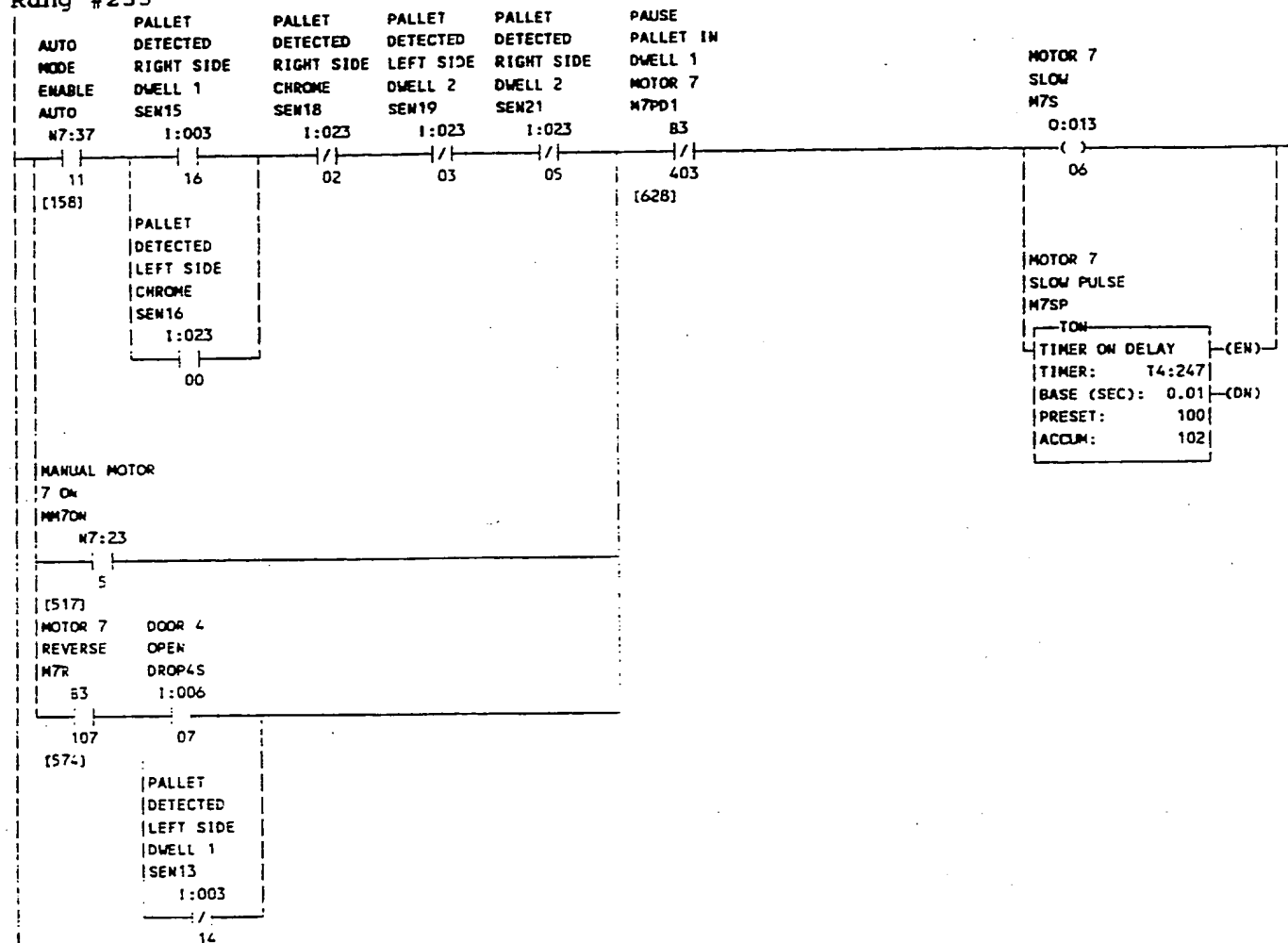
0:012/16 - - - File #5 FAULTS - 3
 - / - - File #2 MAIN_PRGRM - 232
 - () - - File #2 MAIN_PRGRM - 231
 T4:207.TT - - - File #2 MAIN_PRGRM - 230
 Rung #232



T4:227.TT - - - File #2 MAIN_PRGRM - 230

252

Rung #233



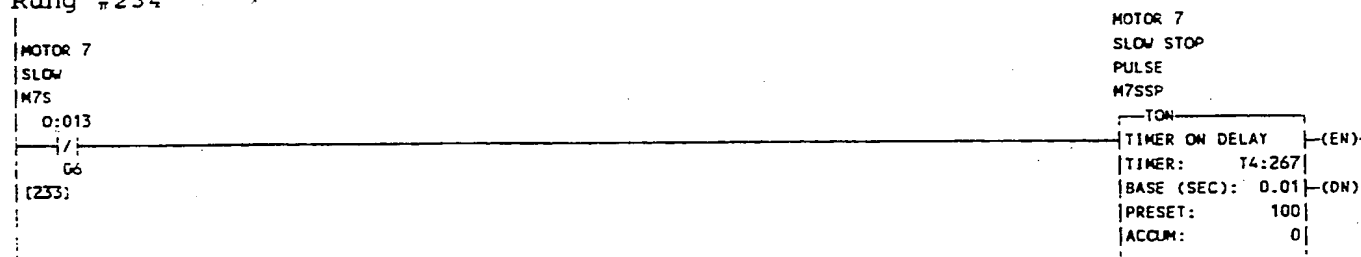
O:013/G6 - - - File #2 MAIN_PRGRM - 235,238,249

- / - - File #2 MAIL PRGRM - 234

-()- - file #2 MAIN PRGRM - 233

T4:247.TI - - - File #2 MAIN_PRGRM - 230

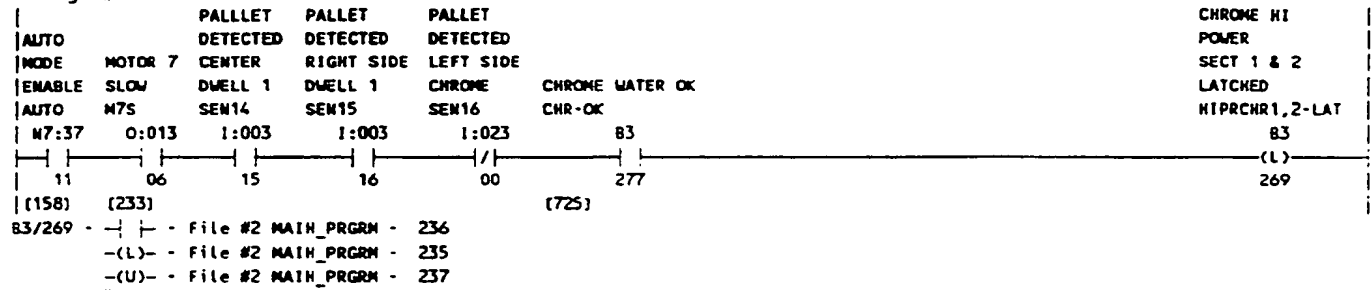
Rung #234



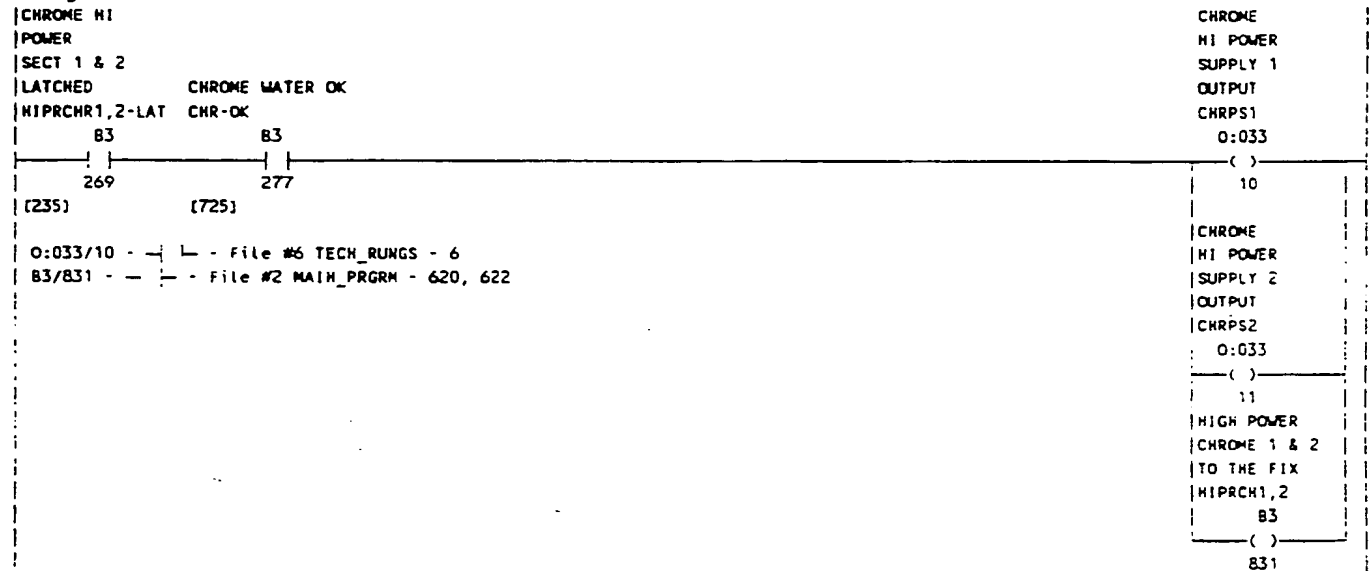
T4:267.TT - - - File #2 MAIN_PRGRM - 230

253

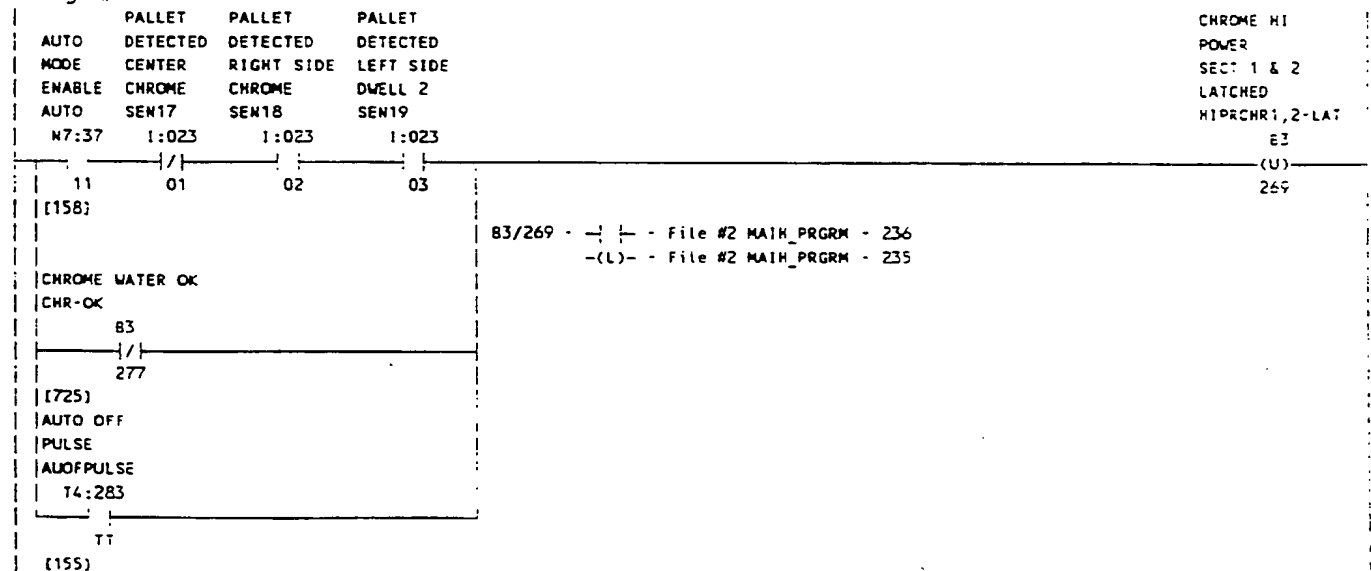
Rung #235



Rung #236

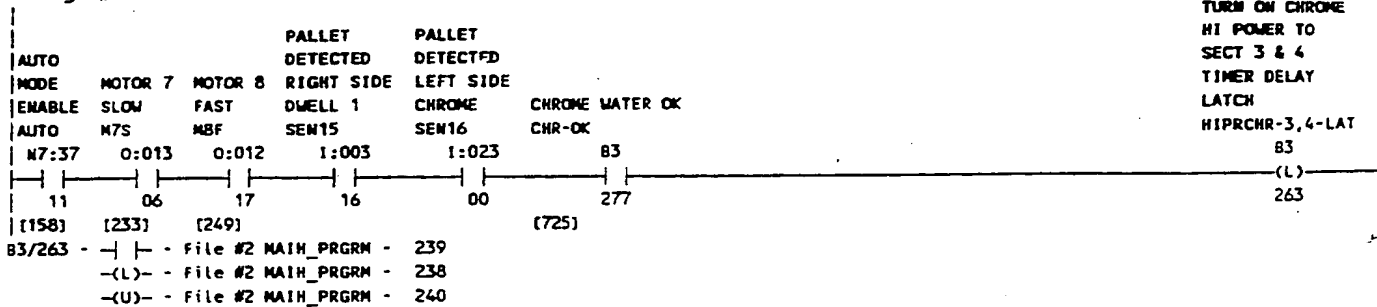


Rung #237

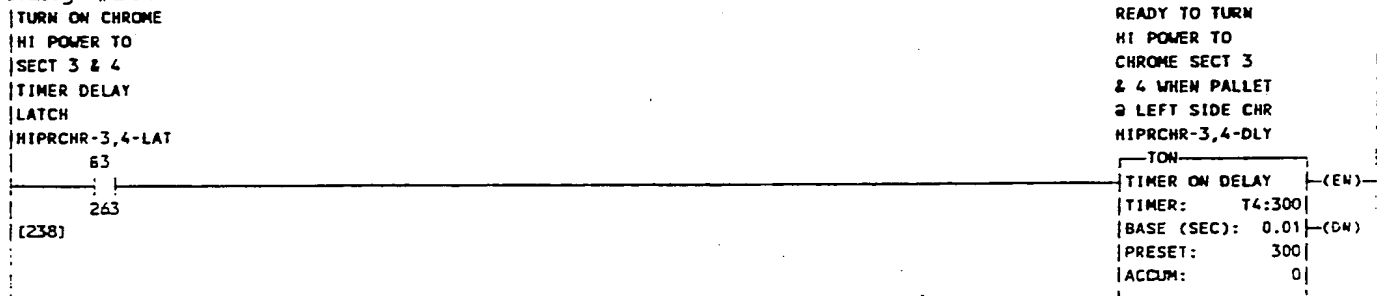


254

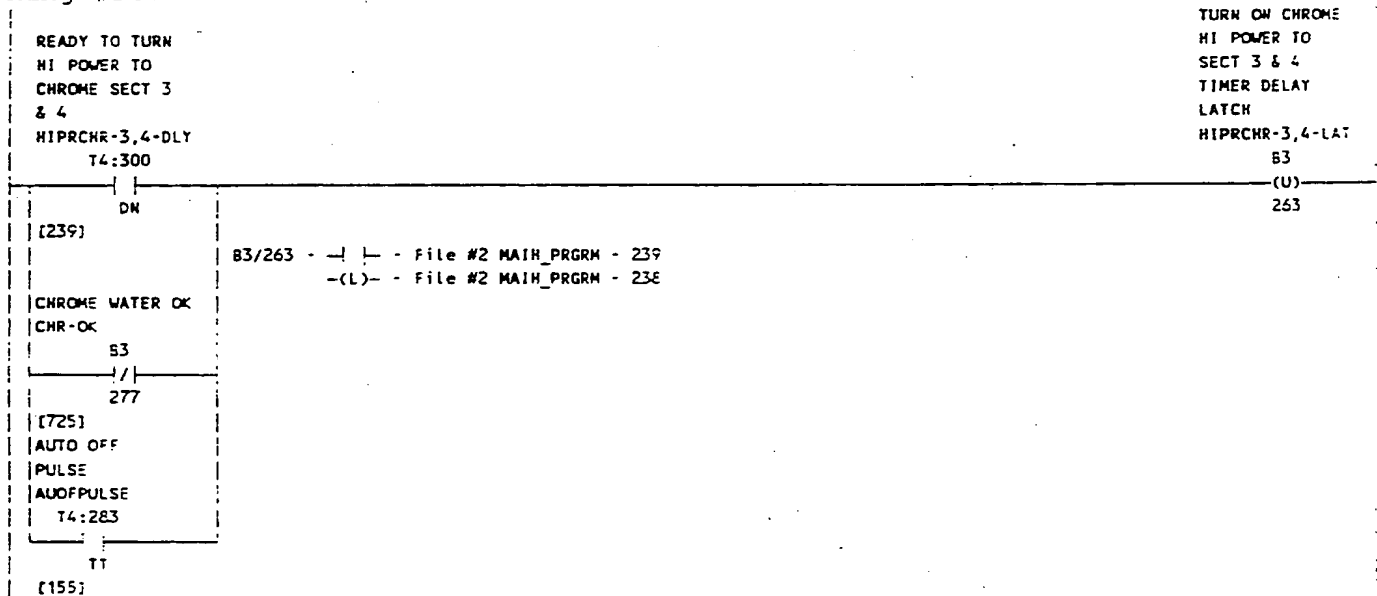
Rung #238



Rung #239



Rung #240



255

Rung #241

READY TO TURN
HI POWER TO
CHROME SECT 3
& 4
HIPRCHR-3,4-DLY
T4:300

HI POWER TO
CHROME SECT
3 & 4
LATCHED
HIPRCHR3,4-LAT
83
(L)
266

DN

[239]

B3/266 - | | - File #2 MAIN_PRGRM - 242
-(L)- - File #2 MAIN_PRGRM - 241
-(U)- - File #2 MAIN_PRGRM - 243

Rung #242

HI POWER TO
CHROME SECT
3 & 4
LATCHED CHROME WATER OK
HIPRCHR3,4-LAT CHR-OK

CHROME
HI POWER
SUPPLY 3
OUTPUT
CHRP3
O:033

83

83

266

277

[241]

[725]

O:033/12 - | | - File #6 TECH_RUNGS - 6
B3/832 - | | - File #2 MAIN_PRGRM - 620, 622

CHROME
HI POWER
SUPPLY 4
OUTPUT
CHRP4
O:033
()
13
HIGH POWER
CHROME 3 & 4
TO THE FIX
HIPRCHR3,4
83
()
832

Rung #243

PALLET PALLET
AUTO DETECTED DETECTED
MODE CENTER RIGHT SIDE
ENABLE DWELL 2 DWELL 2
AUTO SEN20 SEN21
N7:37 I:023 I:023

HI POWER TO
CHROME SECT
3 & 4
LATCHED
HIPRCHR3,4-LAT
83
(U)
266

11

04

05

[158]

B3/266 - | | - File #2 MAIN_PRGRM - 242
-(L)- - File #2 MAIN_PRGRM - 241

CHROME WATER OK
CHR-OK

83

277

[725]

AUTO OFF
PULSE
AUOFFPULSE
T4:283

TT

[155]

256

Rung #244

|PALLET PALLET
 |DETECTED DETECTED
 |LEFT SIDE RIGHT SIDE
 |HEATER 2 HEATER 2
 |SEN10 SEN12
 | 1:003 1:003

CHROME TIMER
 CHR_TMR
 T4:71
 (RES)

T4:71 - RTO - File #2 MAIN_PRGRM - 246
 RES - File #2 MAIN_PRGRM - 244

Rung #245

|PALLET PALLET PALLET
 |DETECTED DETECTED DETECTED
 |LEFT SIDE CENTER RIGHT SIDE
 |DWELL 1 DWELL 1 DWELL 1
 |SEN13 SEN14 SEN15
 | 1:003 1:003 1:003

CHROME COUNTER
 CHR_CNT
 83
 (L)
 90

83/90 - | - File #2 MAIN_PRGRM - 246
 -(L)- - File #2 MAIN_PRGRM - 245
 -(U)- - File #2 MAIN_PRGRM - 247

Rung #246

|CHROME COUNTER
 |CHR_CNT
 | 83
 | 90
 |[245]

CHROME TIMER
 CHR_TMR
 RTC
 RETENTIVE TIMER ON (EN)
 TIMER: T4:71
 BASE (SEC): 1.0 (DN)
 PRESET: 1000
 ACCUM: 2

T4:71 - RTO - File #2 MAIN_PRGRM - 246
 RES - File #2 MAIN_PRGRM - 244

Rung #247

|PALLET PALLET PALLET
 |DETECTED DETECTED DETECTED
 |LEFT SIDE CENTER RIGHT SIDE
 |DWELL 2 DWELL 2 DWELL 2
 |SEN19 SEN20 SEN21
 | 1:023 1:023 1:023

CHROME COUNTER
 CHR_CNT
 83
 (U)
 90

83/90 - | - File #2 MAIN_PRGRM - 246
 -(L)- - File #2 MAIN_PRGRM - 245
 -(U)- - File #2 MAIN_PRGRM - 247

Rung #248

MOTOR 8
SLOW PULSE
M8FP

MOTOR DRIVE
PULSER
MDP

MOTOR 8
INTERRUPT
M8I

T4:208

B3

0:012

TT

299

07

[249]

[14]

MOTOR 8
FAST STOP
PULSE
M8FSP

T4:228

TT

[250]

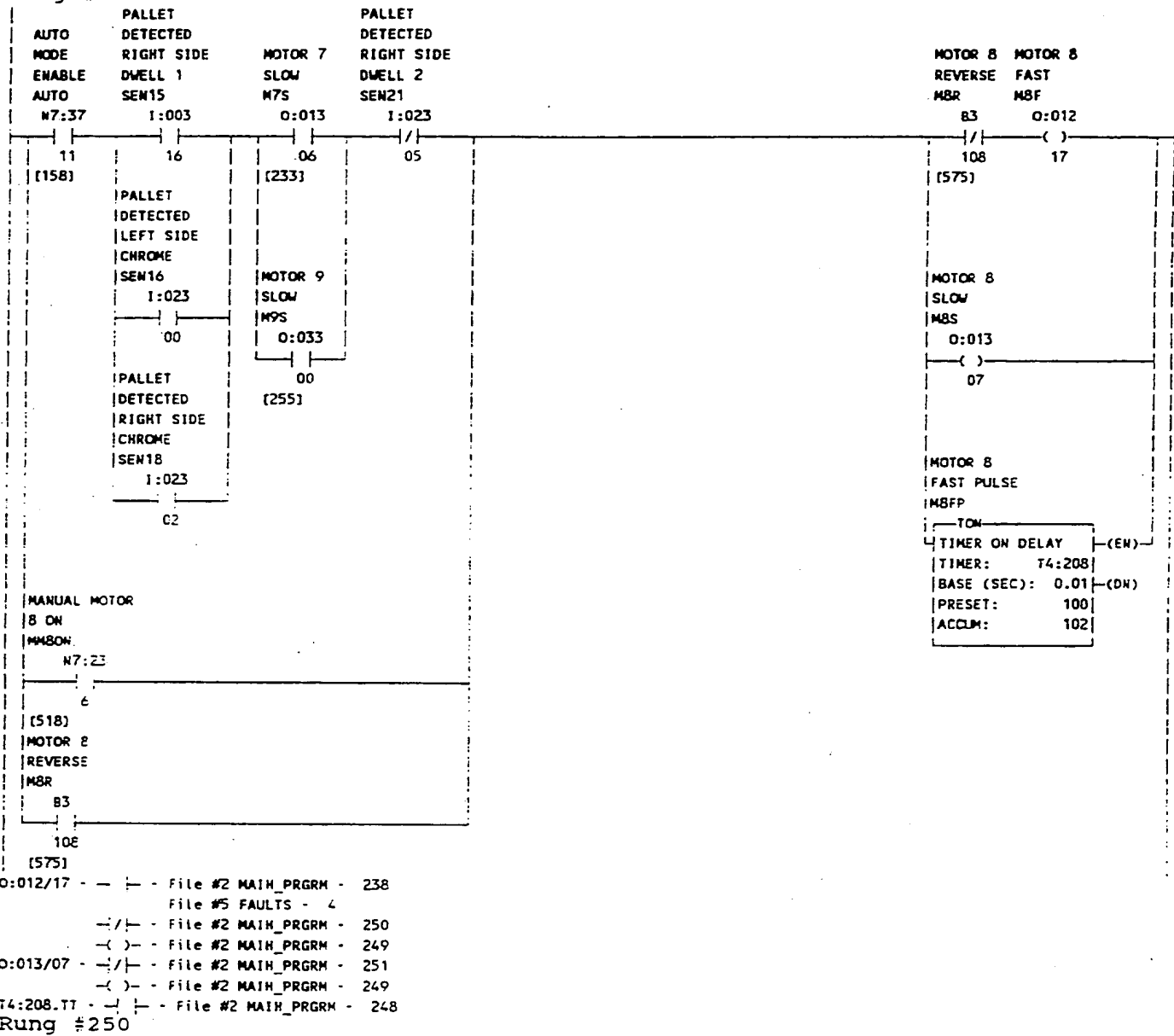
MOTOR 8
SLOW STOP
PULSE
M8SSP

T4:268

TT

[251]

Rung #249



T4:228.TT - | - File #2 MAIN_PRC 248
Rung #251

MOTOR 8
SLOW
MSS

0:013

/|
07

[249]

MOTOR 8
SLOW STOP
PULSE
MSSSP

TON	(EN)
TIMER ON DELAY	
TIMER:	T4:268
BASE (SEC):	0.01 (DN)
PRESET:	100
ACCUM:	0

T4:268.TT - | - File #2 MAIN_PRGRM - 248
Rung #252

MOTOR 9 MOTOR DRIVE
FAST PULSE PULSER
M9FP MDP

T4:209

83

TT

299

[253]

[14]

MOTOR 9
FAST STOP
PULSE
M9FSP

T4:229

TT

[254]

MOTOR 9
SLOW PULSE
M9SP

T4:249

TT

[255]

MOTOR 9
SLOW STOP
PULSE
M9SSP

T4:269

TT

[256]

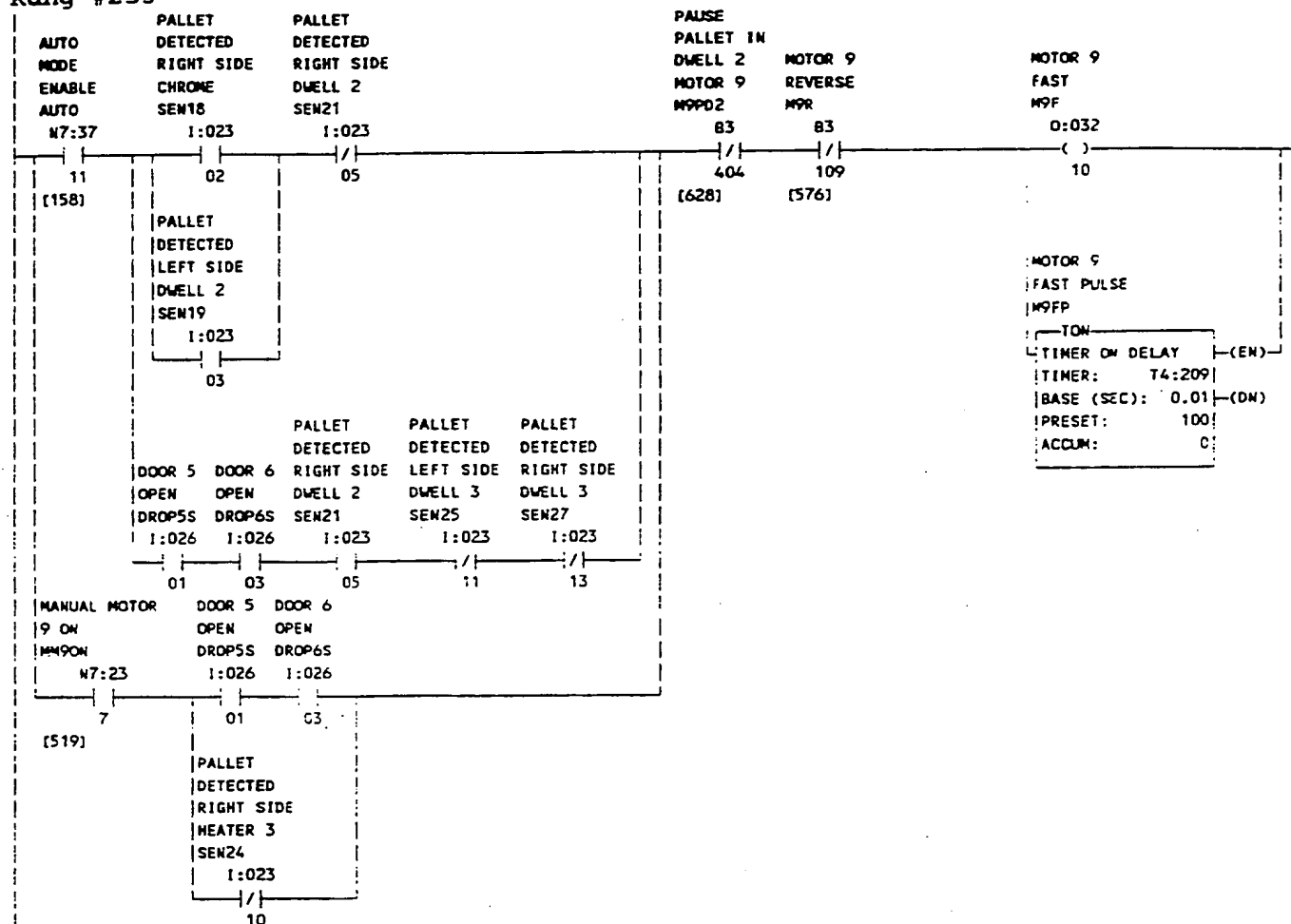
MOTOR 9
INTERRUPT
M9I

0:032

()

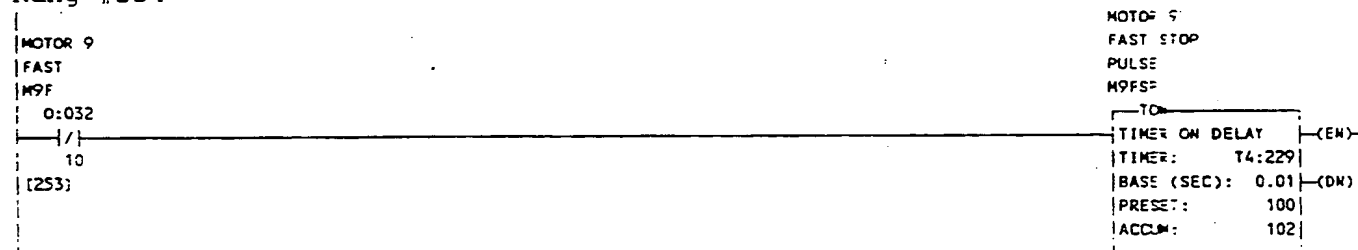
00

Rung #253



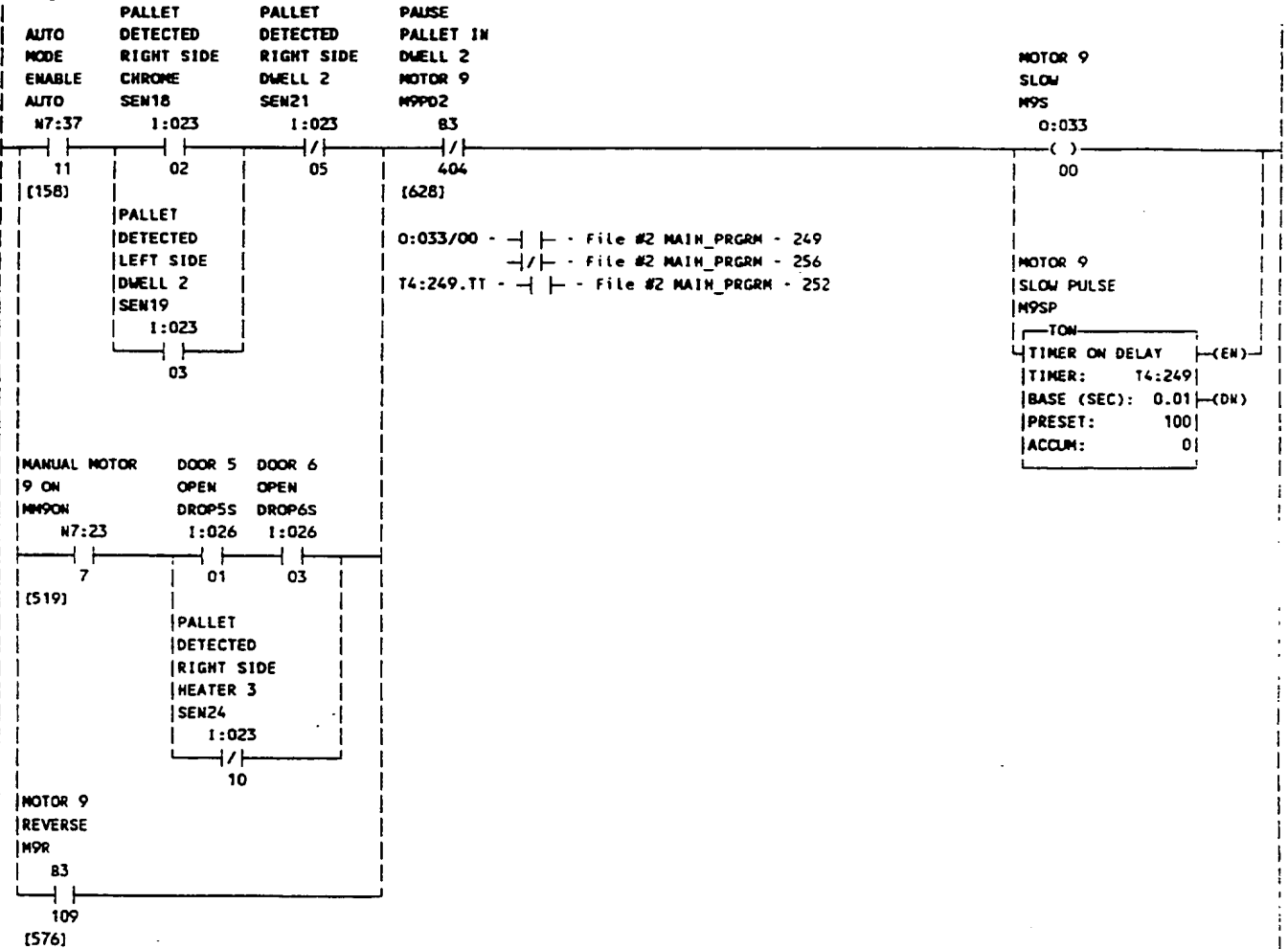
0:032/10 - File #5 FAULTS - 5
 - File #2 MAIN_PRGRM - 254
 - File #2 MAIN_PRGRM - 253
 T4:209.TT - File #2 MAIN_PRGRM - 252

Rung #254

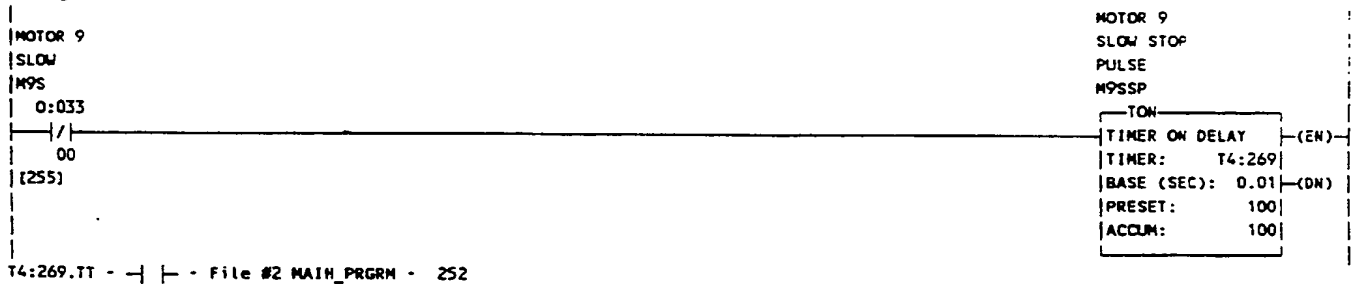


T4:229.TT - File #2 MAIN_PRGRM - 252

Rung #255

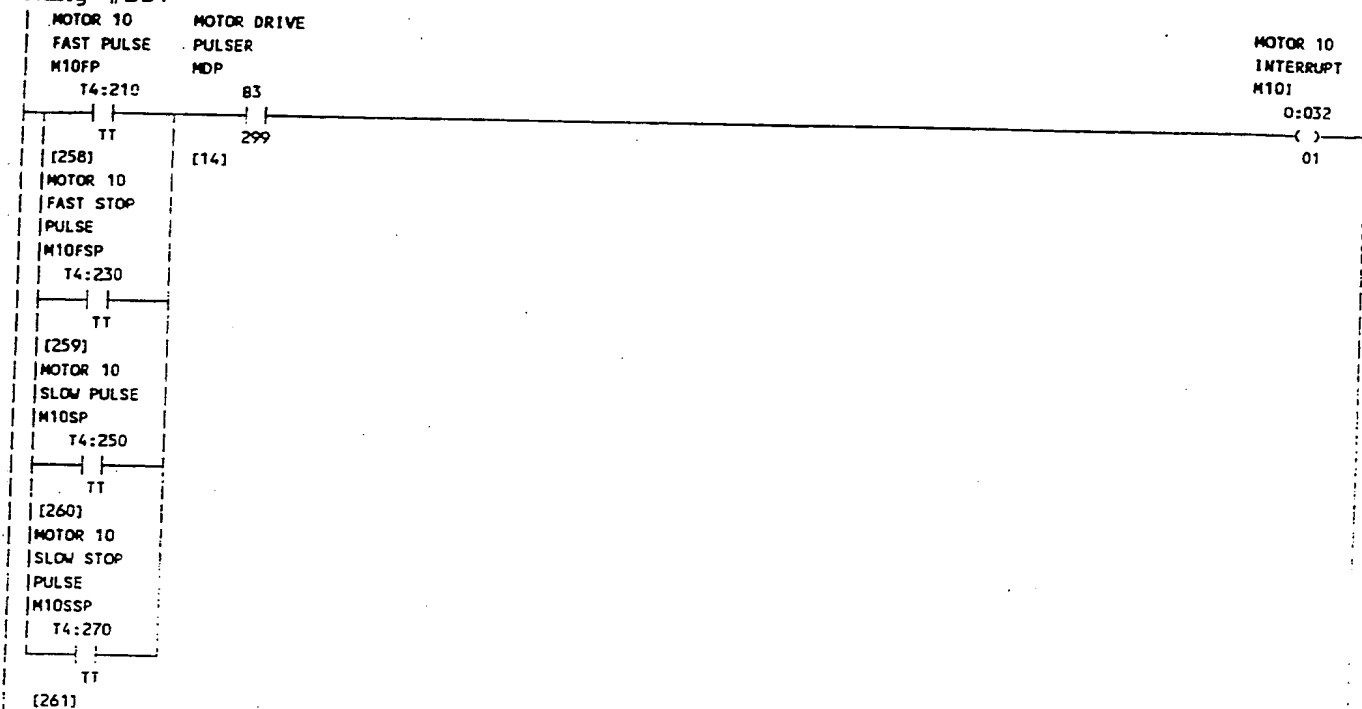


Rung #256



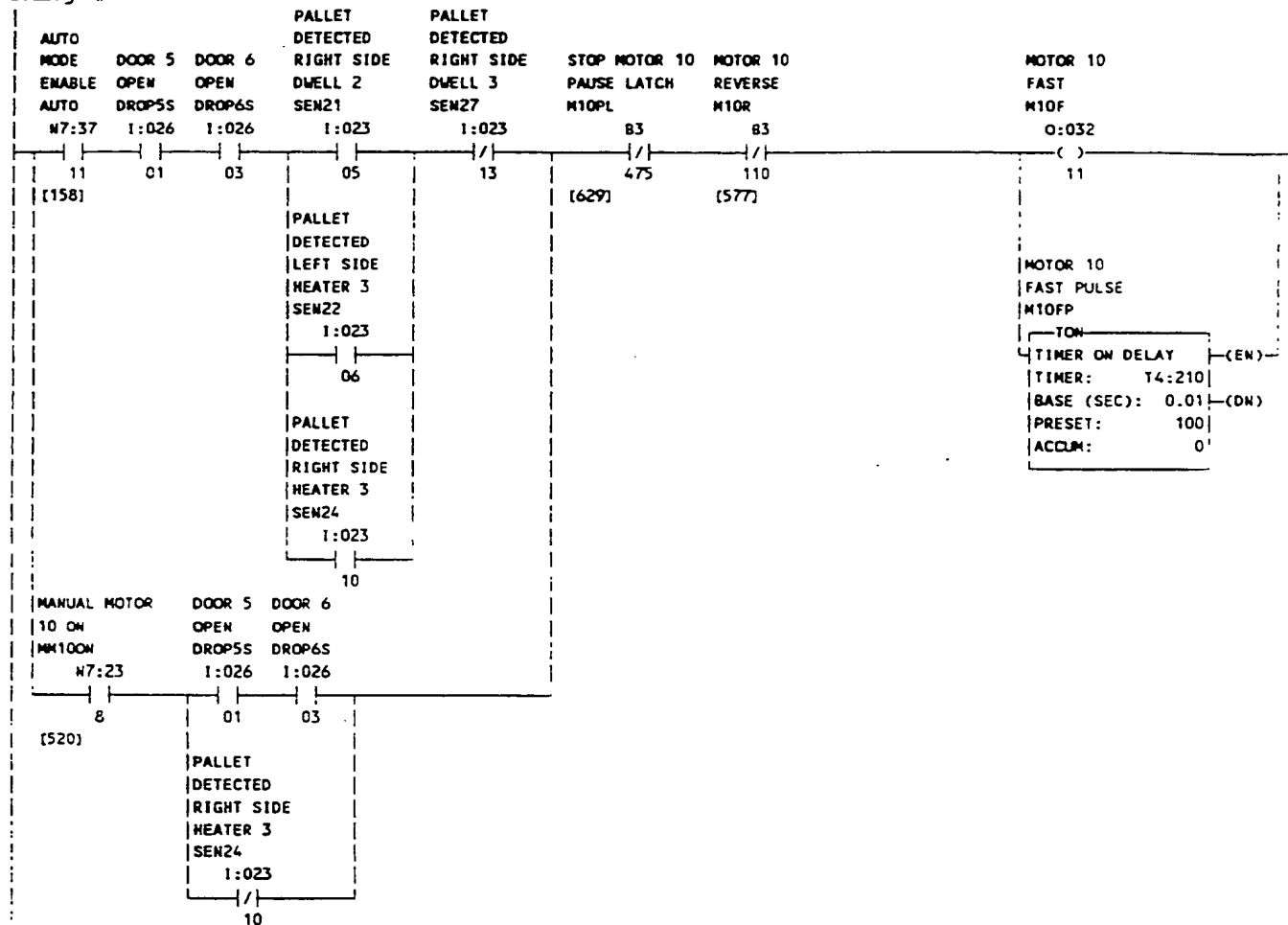
262

Rung #257



263

Rung #258

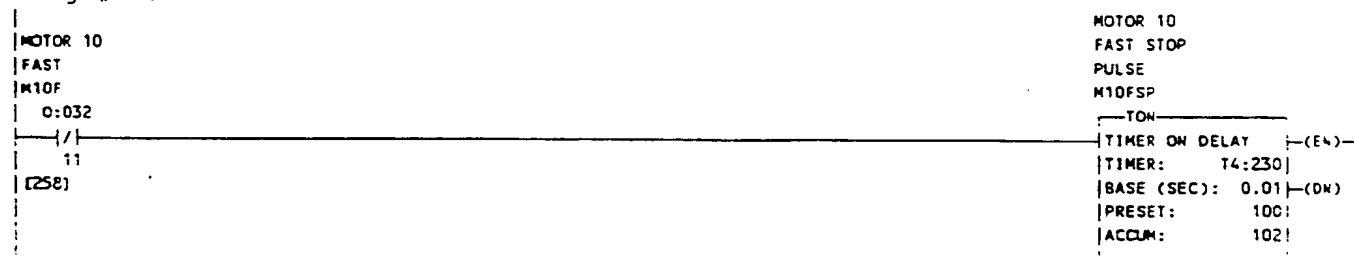


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0:032/11 - - - File #5 FAULTS - 6
           - / - File #2 MAIN_PRGRM - 259
           - ( ) - File #2 MAIN_PRGRM - 258
74:210.YT - - - File #2 MAIN_PRGRM - 257

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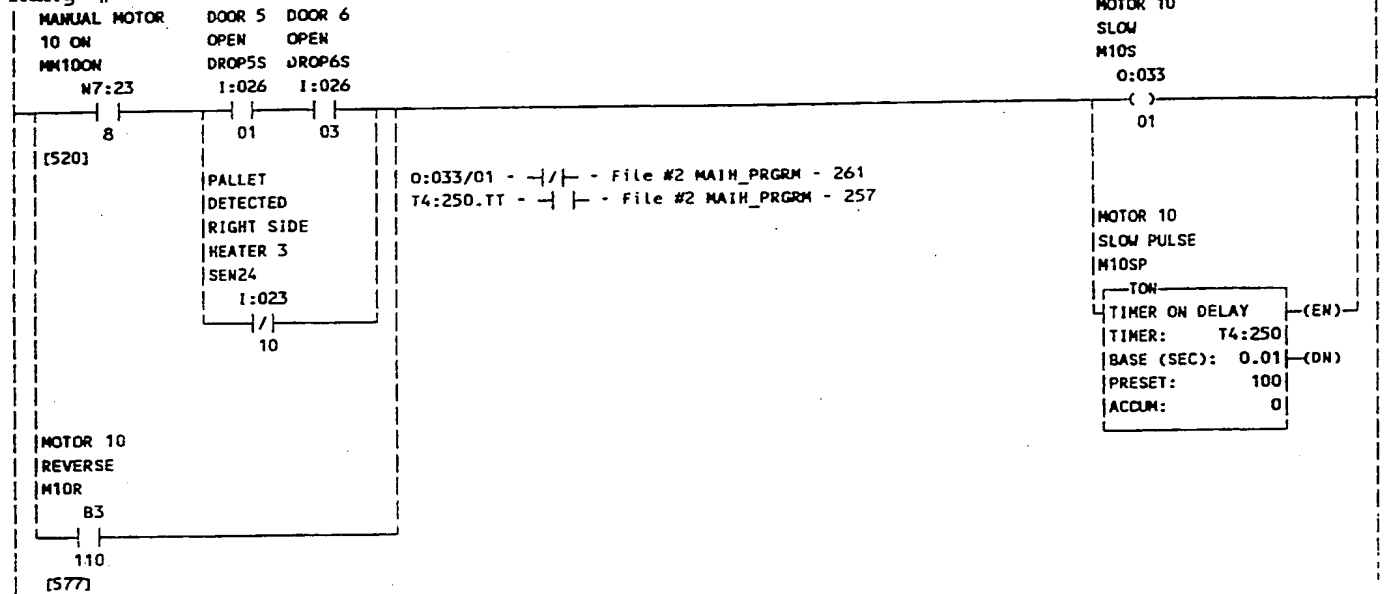
Rung #259



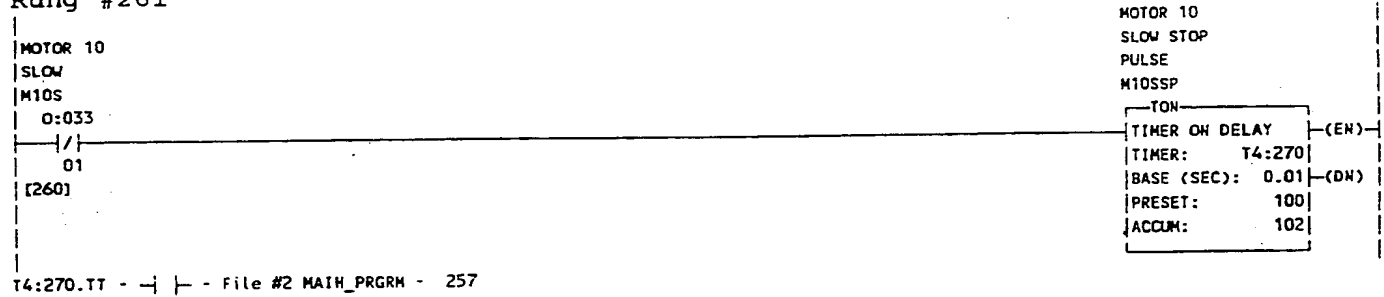
T4:230.TT - - 1 - File #2 MAIN PRGRM - 257

264

Rung #260

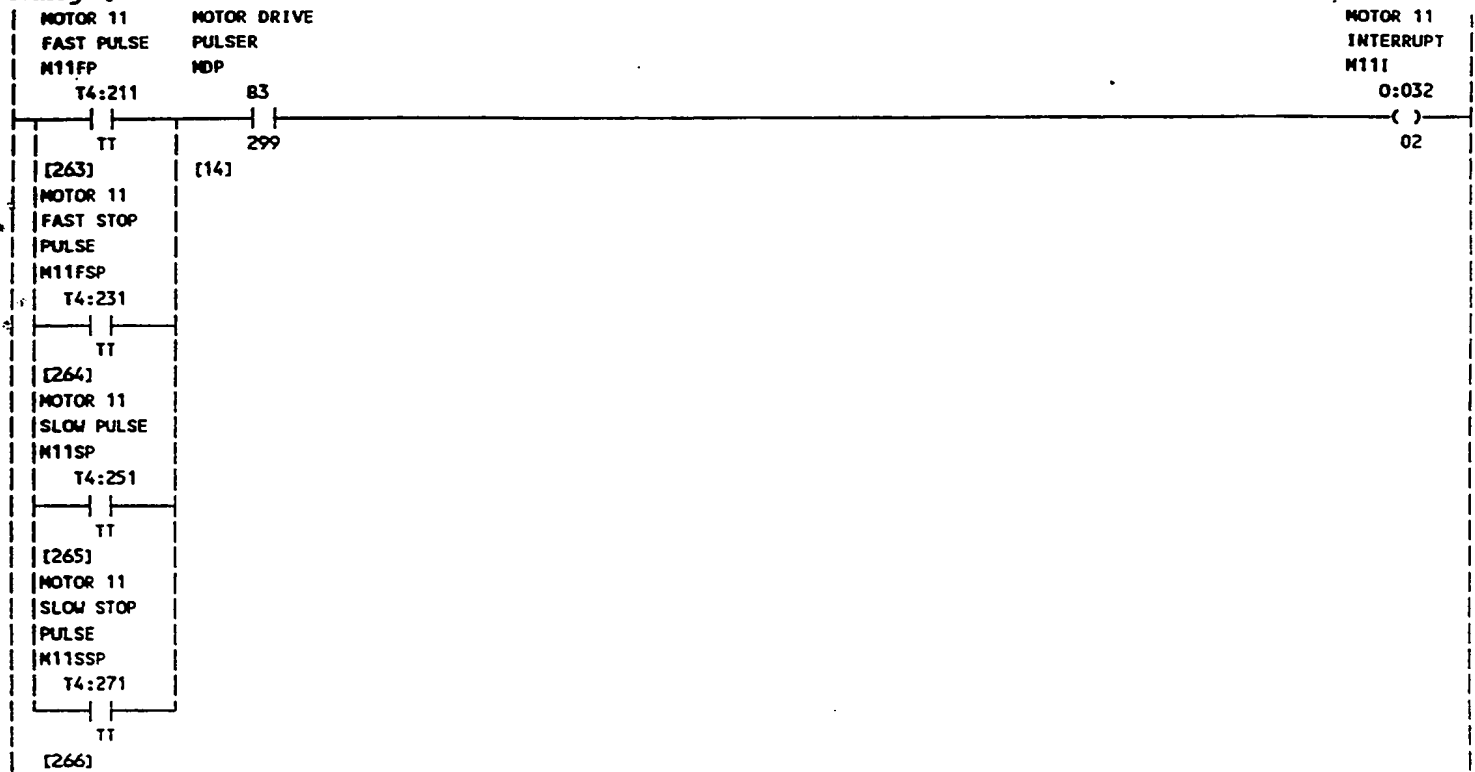


Rung #261



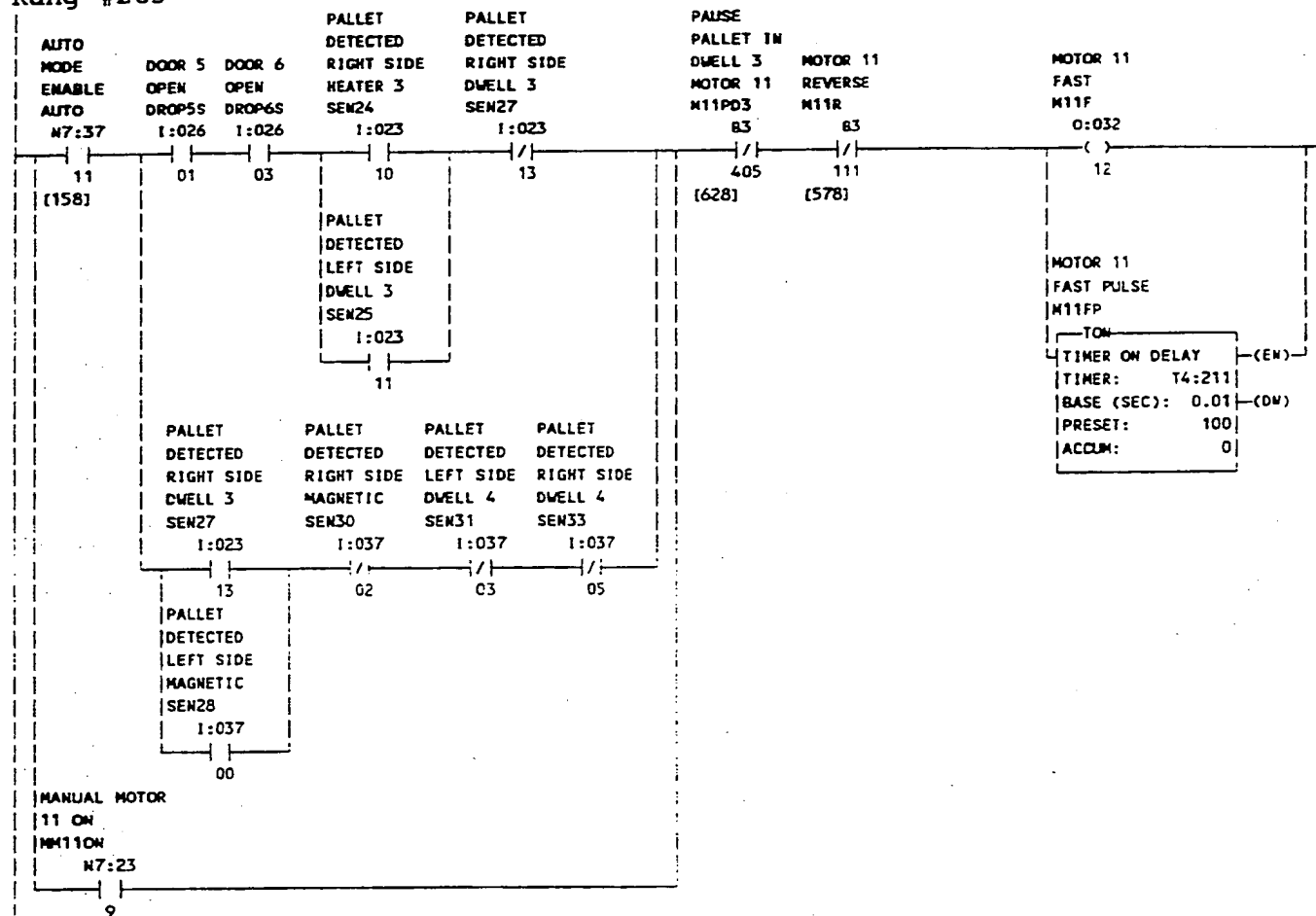
265

Rung #262



266

Rung #263

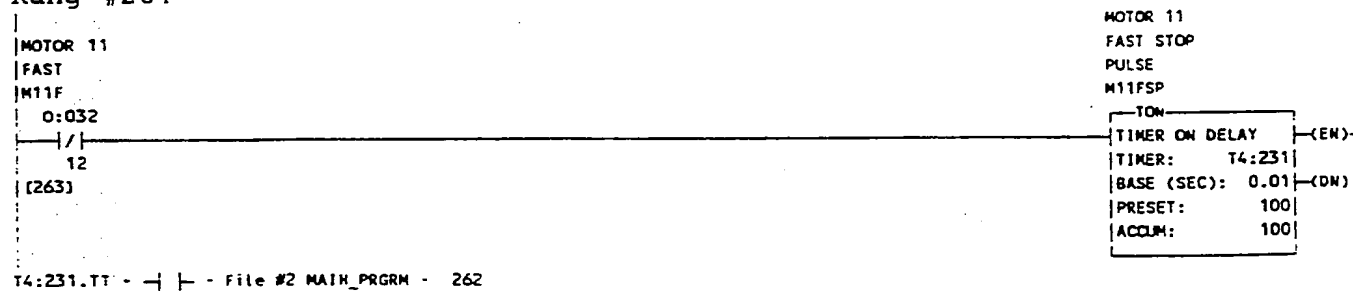


[521]

0:032/12 - | | - File #2 MAIN_PRGRM - 267
 File #5 FAULTS - 6
 -|/| - File #2 MAIN_PRGRM - 264
 -() - File #2 MAIN_PRGRM - 263

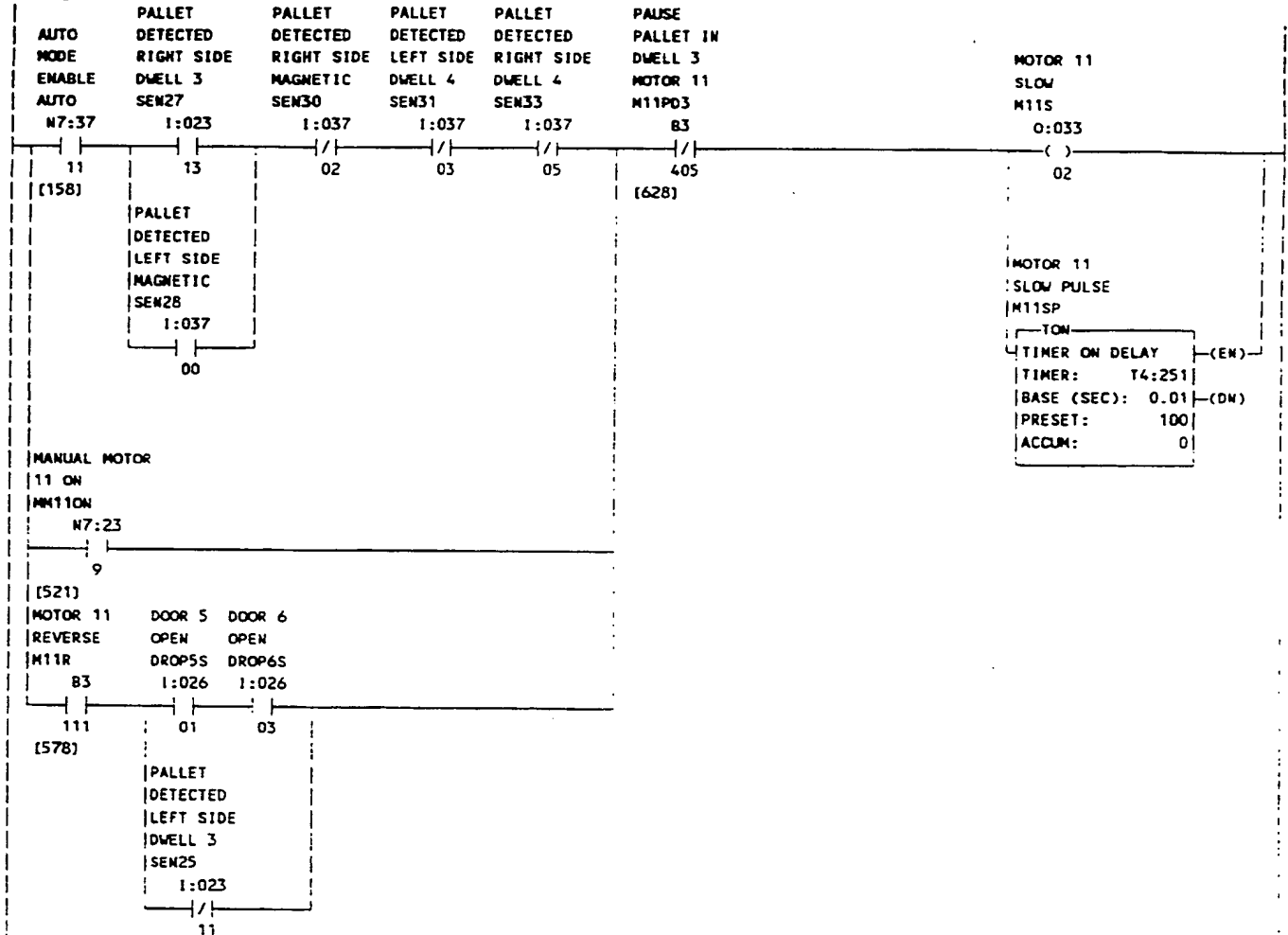
T4:211.TT - | | - File #2 MAIN_PRGRM - 262

Rung #264



267

Rung #265



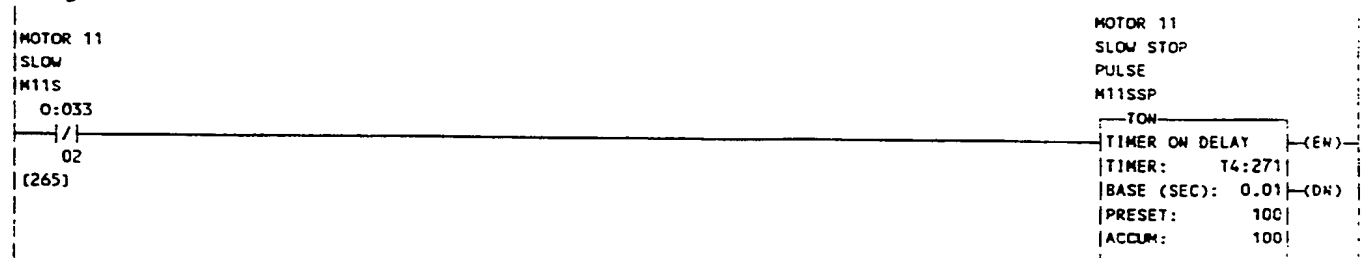
0:033/02 - File #2 MAIN_PRGRM - 270,281

- / - File #2 MAIN_PRGRM - 266

- () - File #2 MAIN_PRGRM - 265

T4:251.TT - File #2 MAIN_PRGRM - 262

Rung #266



T4:271.TT - File #2 MAIN_PRGRM - 262

268

Rung #267

AUTO PALLET PALLET
 MODE DETECTED DETECTED
 MOTOR 11 RIGHT SIDE LEFT SIDE
 ENABLE FAST DWELL 3 MAGNETIC MAG WATER OK
 AUTO M11F SEN27 SEN28 MAG_OK
 T7:37 0:032 1:023 1:037 83
 11 12 13 00 278
 [158] [263] [726]
 83/270 - | | - File #2 MAIN_PRGRM - 268
 -(L)- - File #2 MAIN_PRGRM - 267
 -(U)- - File #2 MAIN_PRGRM - 269

MAGNETIC
 HI POWER
 SECTIONS
 1 AND 2
 LATCHED
 HIPRMAG1,2-LAT
 83
 (L)
 270

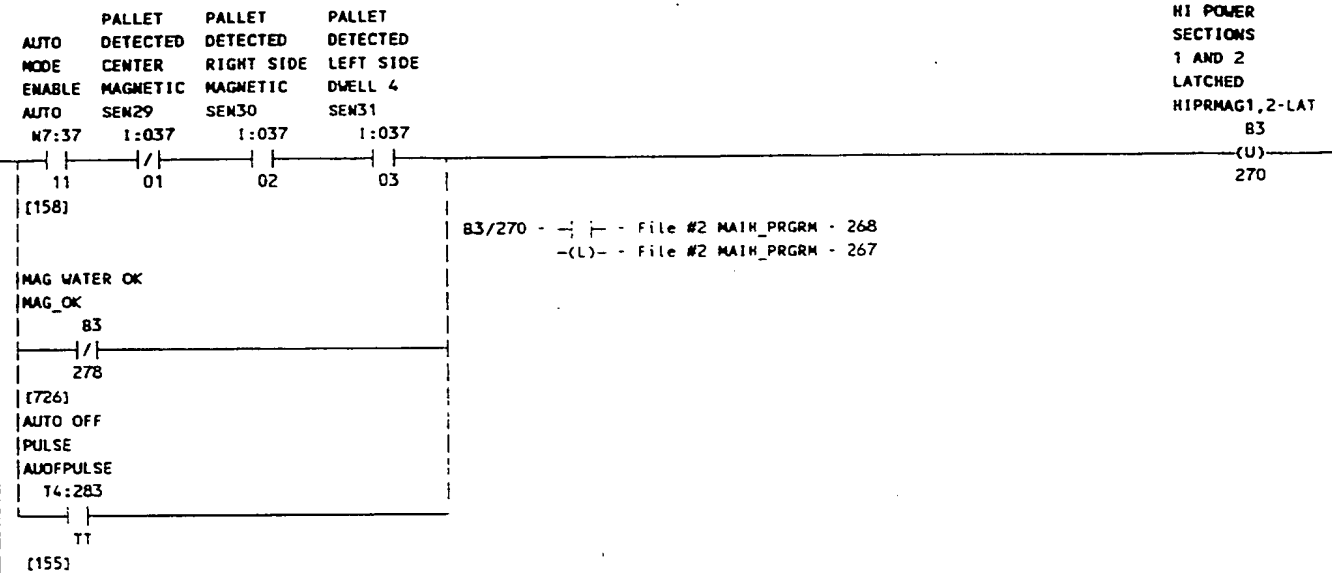
Rung #268

MAGNETIC
 HI POWER
 SECTIONS
 1 AND 2
 LATCHED MAG WATER OK
 HIPRMAG1,2-LAT MAG_OK
 83 83
 270 278
 [267] [726]
 0:033/14 - | | - File #6 TECH_RUNGS - 6
 83/833 - | | - File #2 MAIN_PRGRM - 620, 622

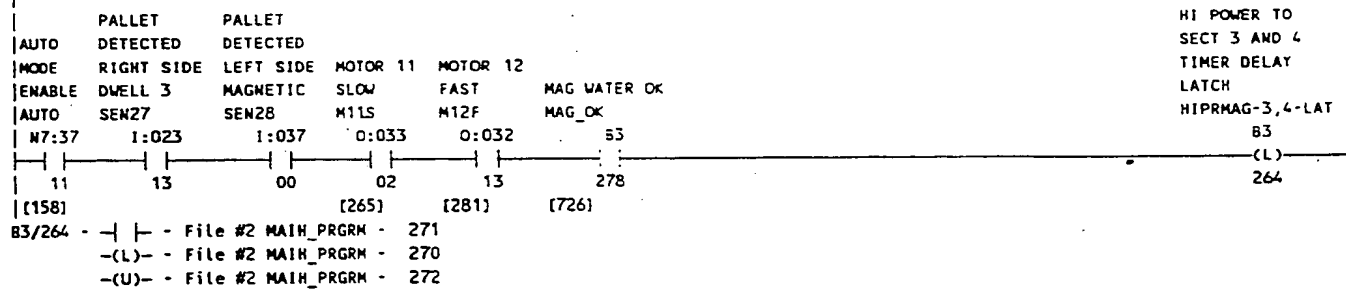
MAGNETIC
 HI POWER
 SUPPLY 1
 OUTPUT
 MAGPS1
 0:033
 ()
 14
 MAGNETIC
 HI POWER
 SUPPLY 2
 OUTPUT
 MAGPS2
 0:033
 ()
 15
 HIGH POWER
 MAG 1 & 2
 TO THE FIX
 HIMAG1,2
 83
 ()
 833

269

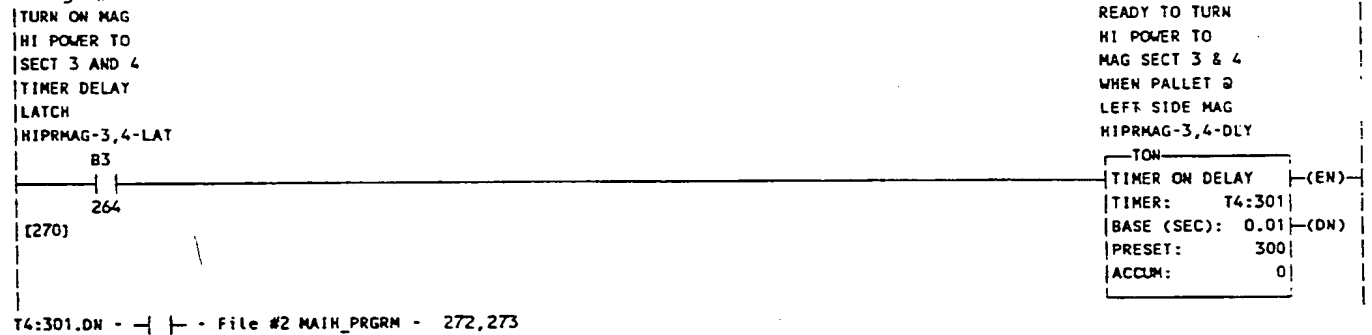
Rung #269



Rung #270



Rung #271



270

Rung #272

READY TO TURN
HI POWER TO
MAG SECT 3 & 4
HIPRMAG-3,4-DLY
T4:301

TURN ON MAG
HI POWER TO
SECT 3 AND 4
TIMER DELAY
LATCH
HIPRMAG-3,4-LAT

B3

(U)
264

DN

[271]

B3/264 - | | - File #2 MAIN_PRGRM - 271
-(L)- - File #2 MAIN_PRGRM - 270

MAG WATER OK
MAG_OK

B3

|/|

278

[726]

AUTO OFF
PULSE
AUOFFPULSE
T4:283

TT

[155]

Rung #273

READY TO TURN
HI POWER TO
MAG SECT 3 & 4
HIPRMAG-3,4-DLY
T4:301

HI POWER TO
MAGNETIC
SECTIONS
3 AND 4
LATCHED
HIPRMAG3,4-LAT

B3

(L)
267

DN

[271]

B3/267 - | | - File #2 MAIN_PRGRM - 274
-(L)- - File #2 MAIN_PRGRM - 273
-(U)- - File #2 MAIN_PRGRM - 275

271

Rung #274

HI POWER TO

MAGNETIC

SECTIONS

3 AND 4

LATCHED

HIPRMAG3,4-LAT

MAG WATER OK

MAG_OK

B3

B3

267

278

[273]

[261]

0:063/10 - | | - File #6 TECH_RUNGS - 6

B3/B34 - | | - File #2 MAIN_PRGRM - 620, 622

MAGNETIC

HI POWER

SUPPLY 3

OUTPUT

MAGPS3

0:063

()

10

MAGNETIC

HI POWER

SUPPLY 4

OUTPUT

MAGPS4

0:063

()

11

HIGH POWER

MAG 3 & 4

TO THE FIX

HIPRMAG3,4

B3

()

B34

Rung #275

PALLET PALLET
 AUTO DETECTED DETECTED
 MODE MIDDLE RIGHT SIDE
 ENABLE DWELL 4 DWELL 4
 AUTO SEN32 SEN33
 M7:37 1:037 1:037

11

04

05

[158]

B3/267 - | | - File #2 MAIN_PRGRM - 274

-(L)- - File #2 MAIN_PRGRM - 273

MAG WATER OK

MAG_OK

B3

/

278

[261]

AUTO OFF

PULSE

AUOFFPULSE

T4:283

TT

[155]

Rung #276

PALLET PALLET
 DETECTED DETECTED
 LEFT SIDE RIGHT SIDE
 HEATER 3 HEATER 3
 SEN22 SEN24
 1:023 1:023

06

10

T4:72 - RTO - File #2 MAIN_PRGRM - 278

HI POWER TO

MAGNETIC

SECTIONS

3 AND 4

LATCHED

HIPRMAG3,4-LAT

B3

(U)

267

MAGNETIC TIME

MAG_TMR

T4:72

[RES]

272

RES - File #2 MAIN_PRGRM - 1

Rung #277

PALLET	PALLET	PALLET
DETECTED	DETECTED	DETECTED
LEFT SIDE	CENTER	RIGHT SIDE
DWELL 3	DWELL 3	DWELL 3
SEN25	SEN26	SEN27
1:023	1:023	1:023

MAGNETIC
TRANSIT
MAG_TRAN
83

83/91 - | | - File #2 MAIN_PRGRM - 278
 -(L)- - File #2 MAIN_PRGRM - 277
 -(U)- - File #2 MAIN_PRGRM - 279

Rung #278

MAGNETIC
TRANSIT
MAG_TRAN
83

MAGNETIC TIMER

MAG_TMR

RTO

RETENTIVE TIMER ON (EN)

TIMER: T4:72

BASE (SEC): 1.0 (DN)

PRESET: 1000

ACCUM: 79

T4:72 - RTO - File #2 MAIN_PRGRM - 278

RES - File #2 MAIN_PRGRM - 276

Rung #279

PALLET	PALLET	PALLET
DETECTED	DETECTED	DETECTED
LEFT SIDE	MIDDLE	RIGHT SIDE
DWELL 4	DWELL 4	DWELL 4
SEN31	SEN32	SEN33
1:037	1:037	1:037

MAGNETIC
TRANSIT
MAG_TRAN
63

83/91 - | | - File #2 MAIN_PRGRM - 278
 -(L)- - File #2 MAIN_PRGRM - 277
 -(U)- - File #2 MAIN_PRGRM - 279

Rung #280

MOTOR 12	MOTOR DRIVE
SLOW PULSE	PULSER
M12SP	MDP

MOTOR 12
INTERRUPT
M12I

T4:212	83	0:032
TT	299	C3

[281] [14]

MOTOR 12

FAST STOP

PULSE

M12FSP

T4:232

TT

[282]

MOTOR 12

SLOW STOP

PULSE

M12SSP

T4:272

TT

[283]

T4:232.TT - - File #2 MAIN_PRGRM 280
Rung #283

MOTOR 12
SLOW
M12S

0:033

[281]

MOTOR 12
SLOW STOP
PULSE
M12SSP

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:272
BASE (SEC):	0.01 (DN)
PRESET:	100
ACCUM:	102

T4:272.TT - - File #2 MAIN_PRGRM - 280
Rung #284

MOTOR 13 MOTOR DRIVE
FAST PULSE PULSER
M13FP MDP

T4:213

83

[285]

MOTOR 13

FAST STOP

PULSE

M13FSP

T4:233

TT

[286]

MOTOR 13

SLOW PULSE

M13SP

T4:253

TT

[287]

MOTOR 13

SLOW STOP

PULSE

M13SSP

T4:273

TT

[288]

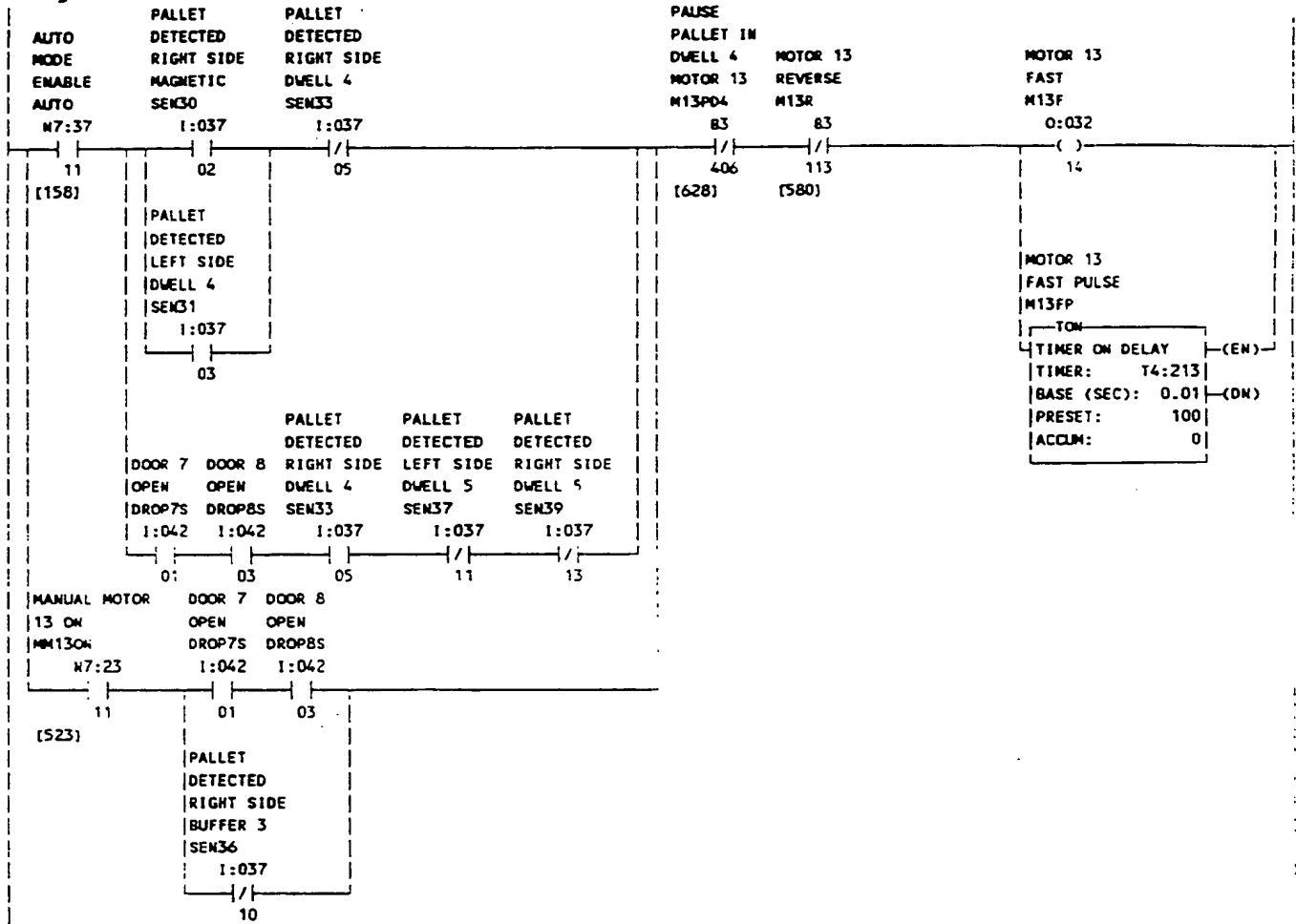
MOTOR 13
INTERRUPT
M13I

0:032

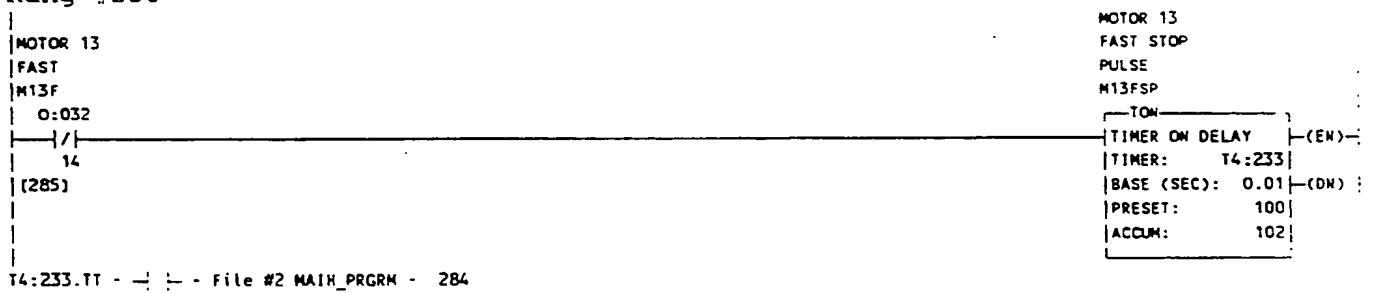
()

04

Rung #285



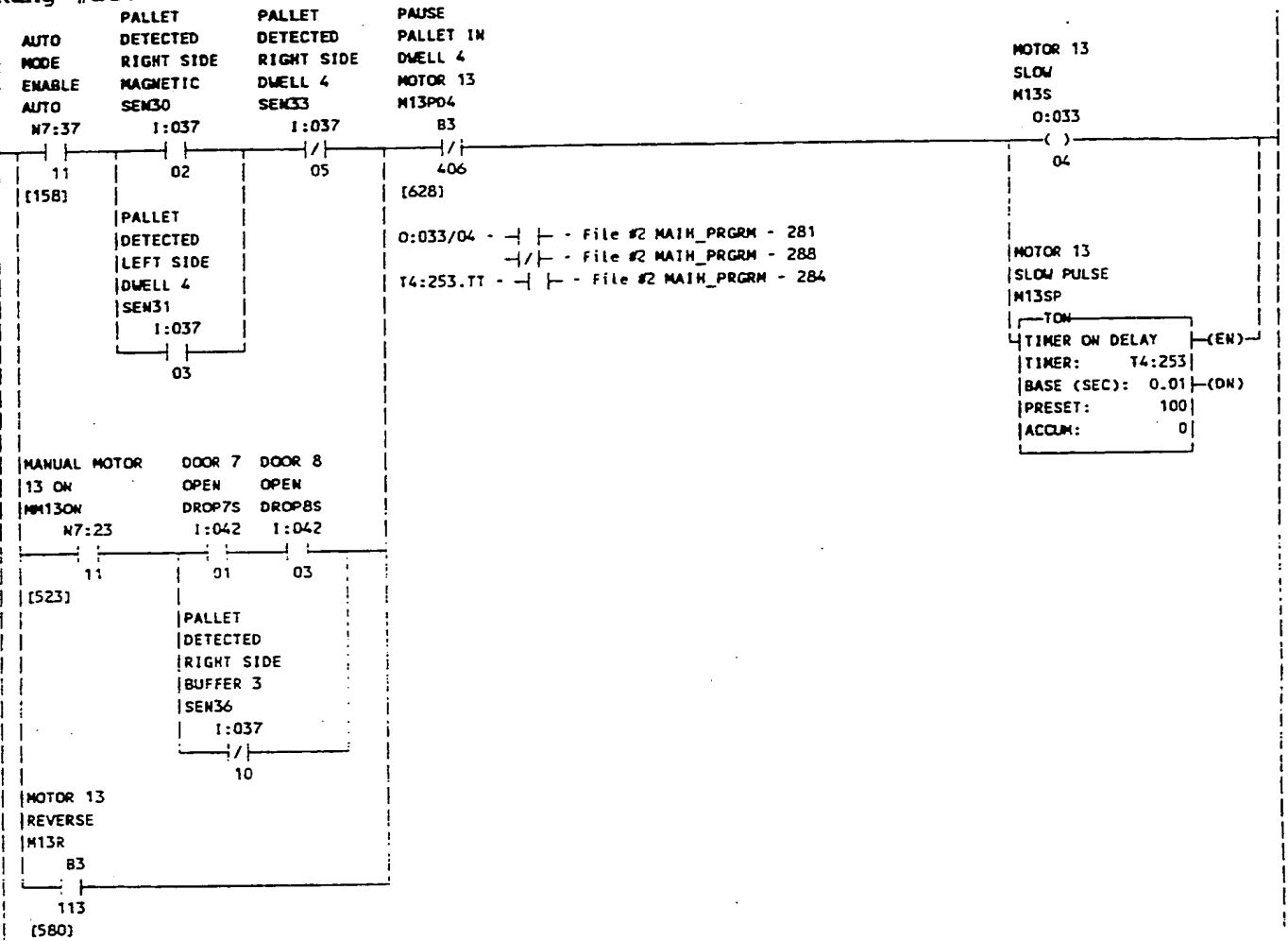
O:032/14 - File #5 FAULTS - 8
 - File #2 MAIN_PRGRM - 286
 - File #2 MAIN_PRGRM - 285
 T4:213.TT - File #2 MAIN_PRGRM - 284
 Rung #286



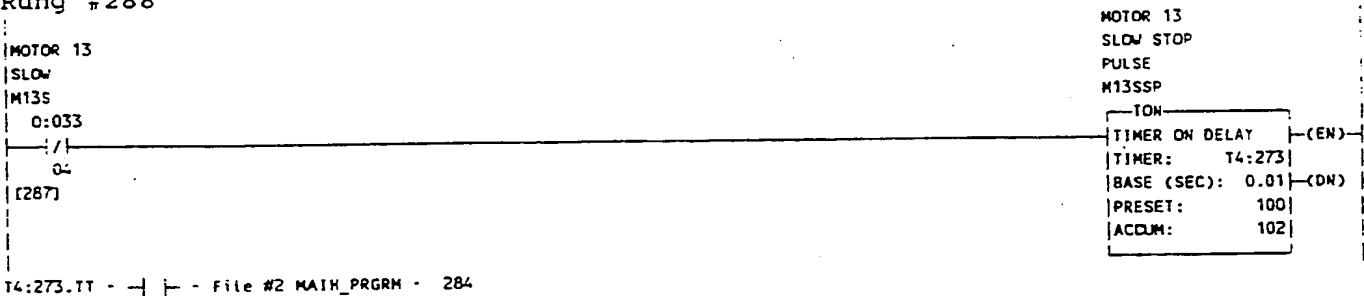
T4:233.TT - File #2 MAIN_PRGRM - 284

276

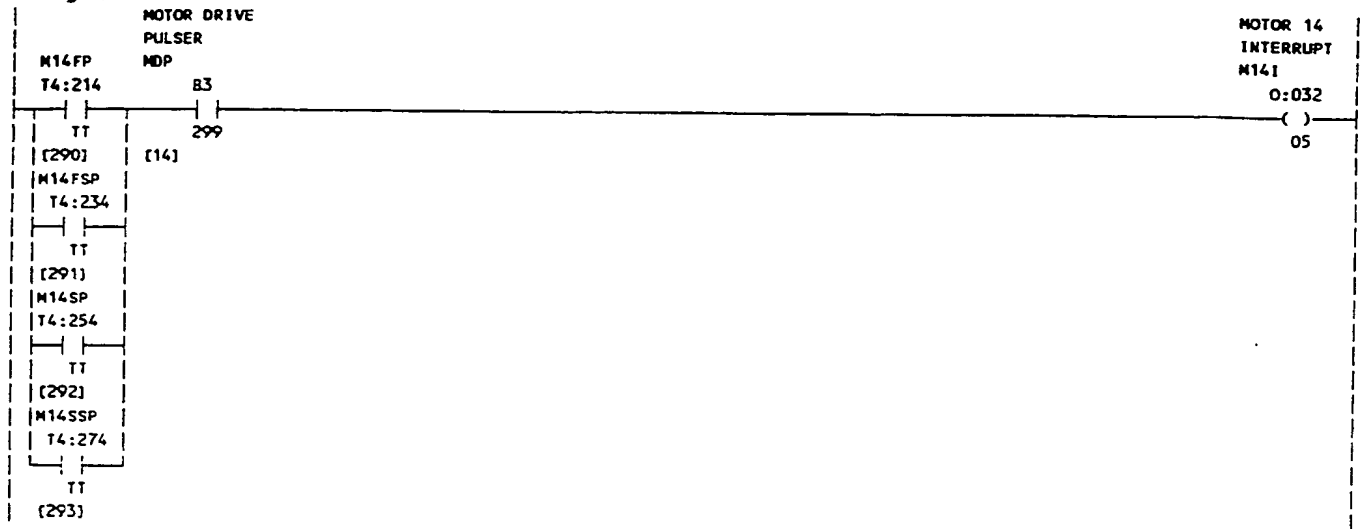
Rung #287



Rung #288

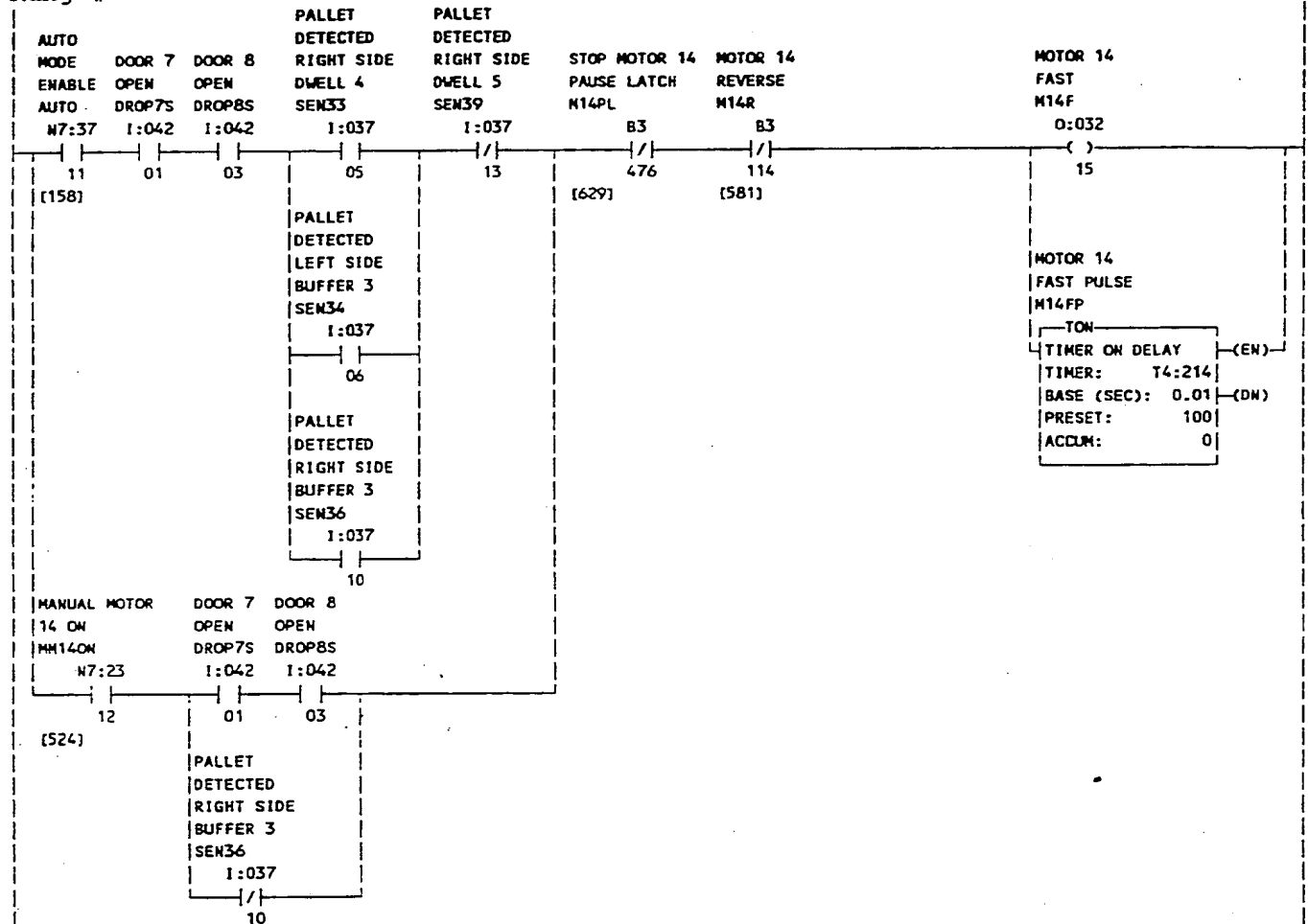


Rung #289

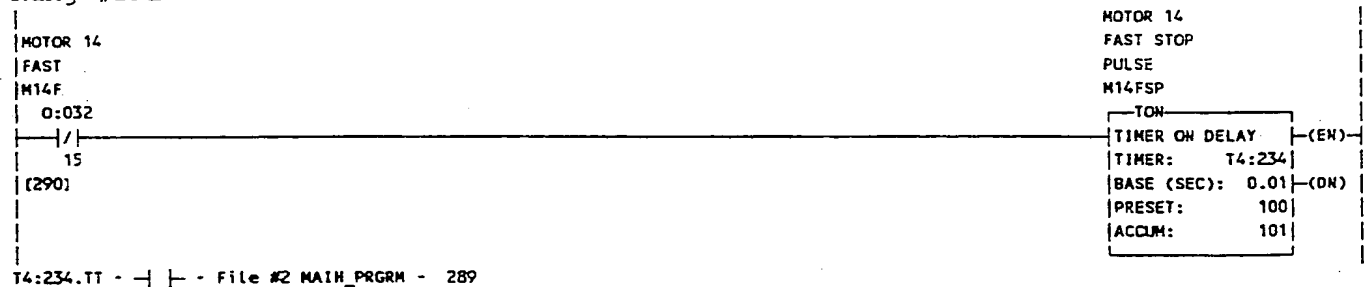


278

Rung #290



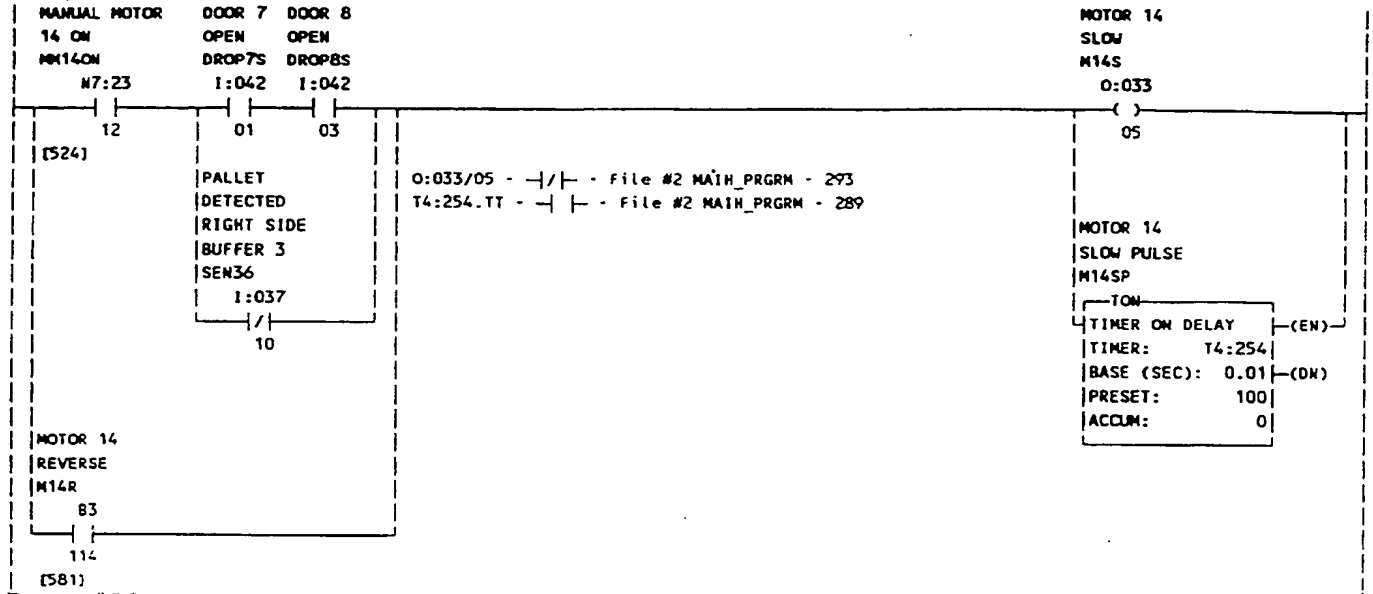
O:032/15 - | | - File #5 FAULTS - 9
 -|/| - File #2 MAIN_PRGRM - 291
 - () - File #2 MAIN_PRGRM - 290
 T4:214.TT - | | - File #2 MAIN_PRGRM - 289
 Rung #291



T4:234.TT - | | - File #2 MAIN_PRGRM - 289

279

Rung #292

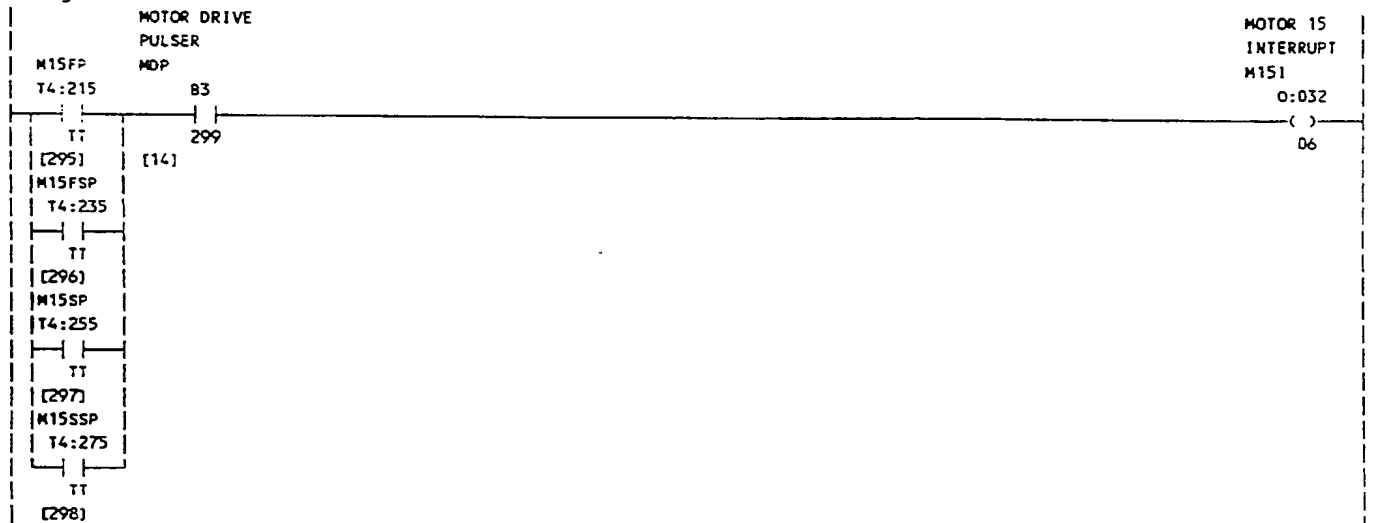


Rung #293

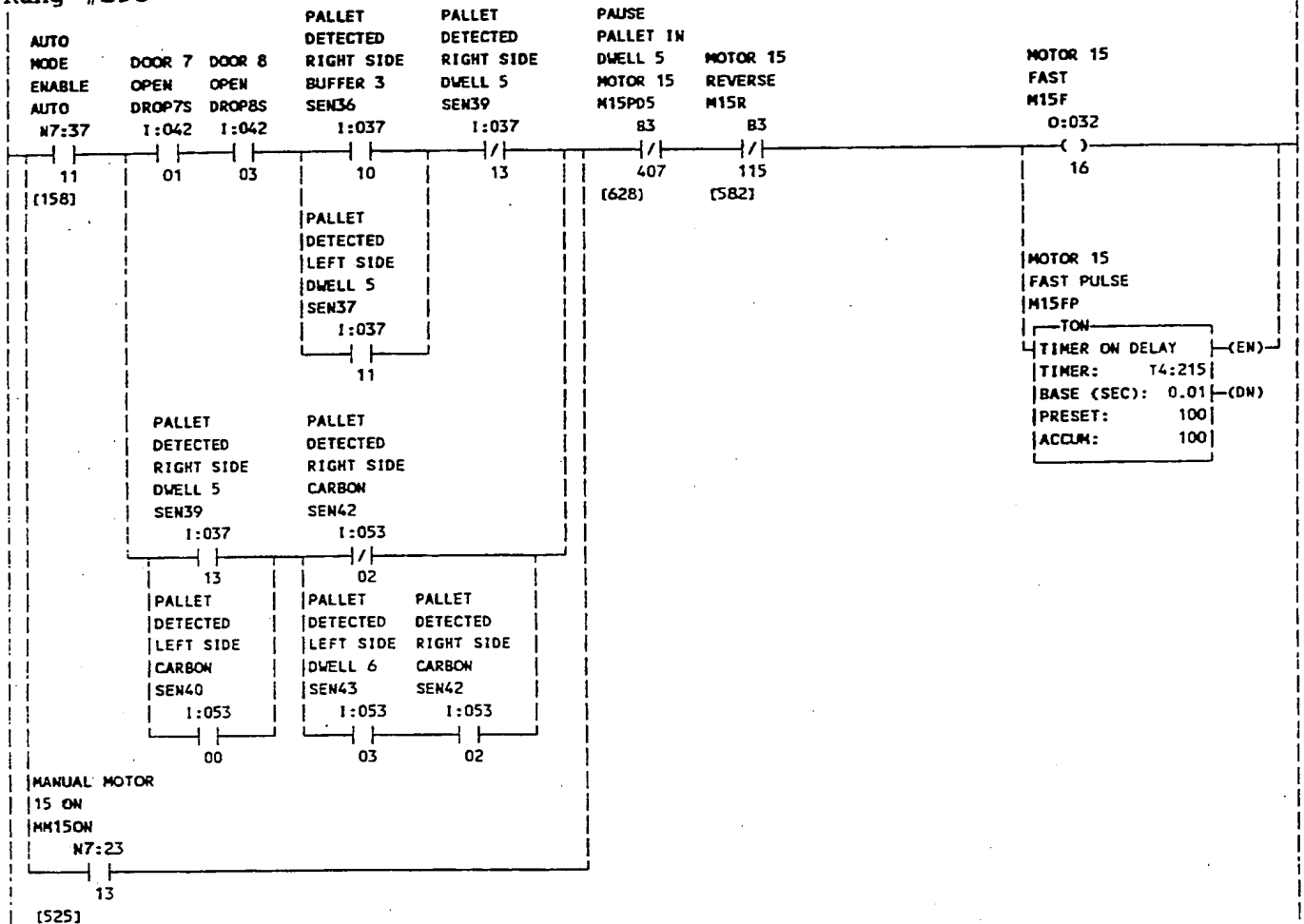


T4:274.TT - | | - File #2 MAIN_PRGRM - 289

Rung #294



Rung #295



MANUAL MOTOR 15 ON (M15ON, N7:23)

13

[525]

0:032/16 - File #5 FAULTS - 9

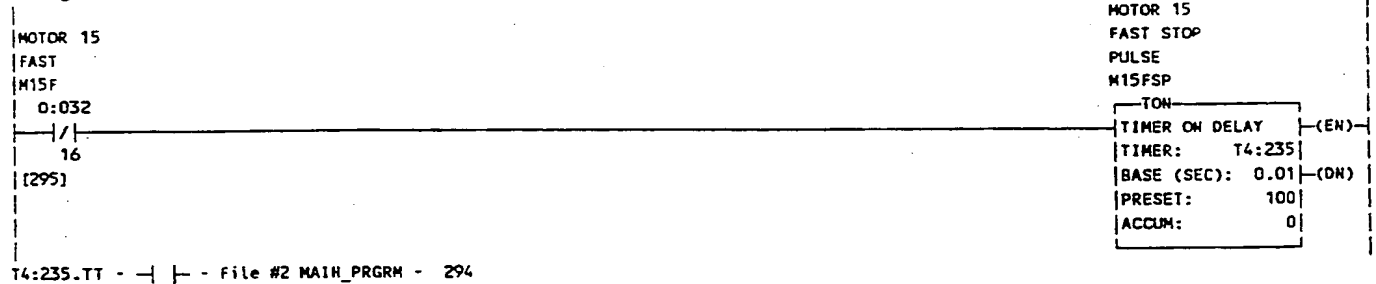
File #2 MAIN_PRGRM - 296

File #2 MAIN_PRGRM - 295

File #2 MAIN_PRGRM - 294

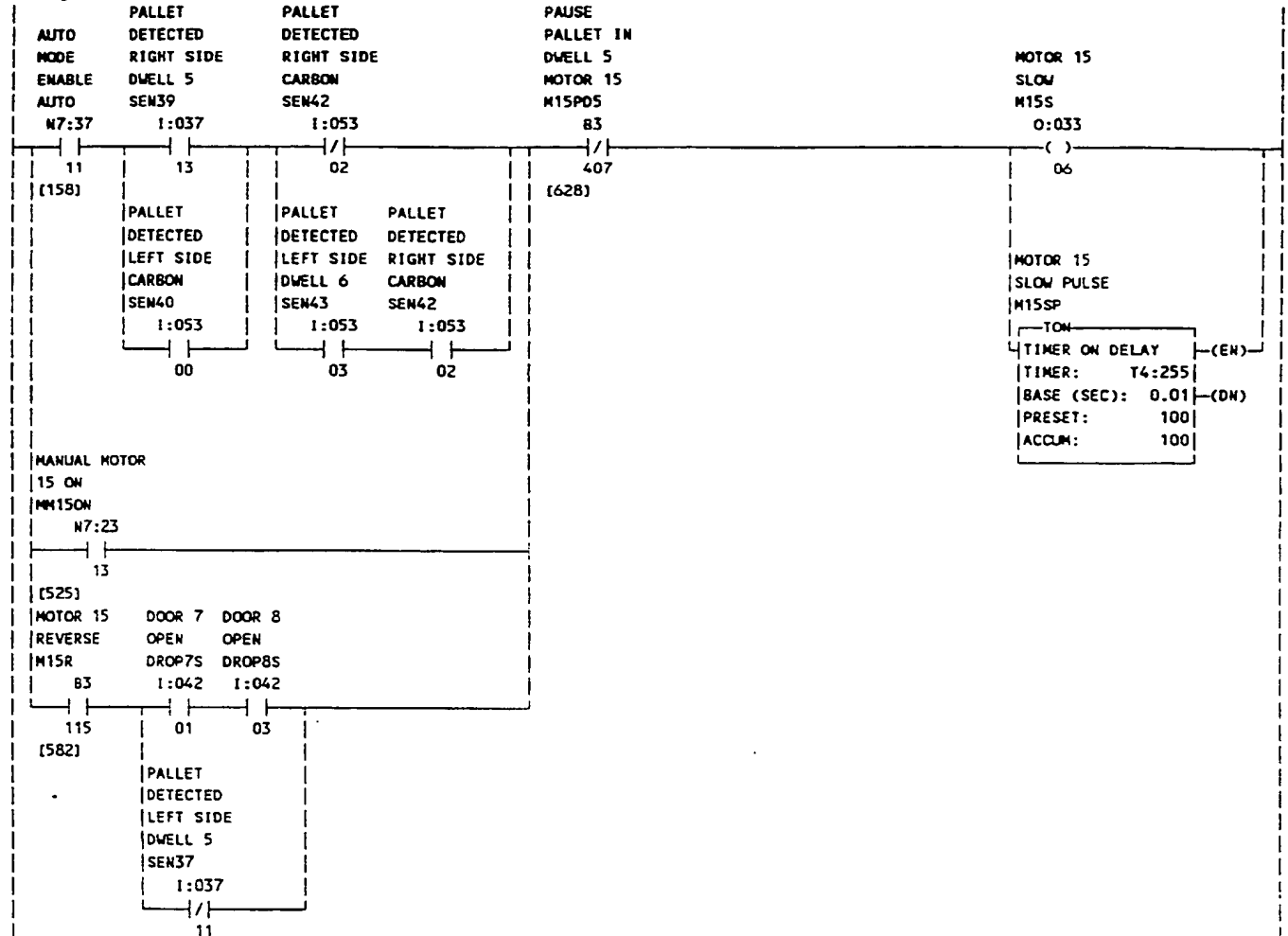
T4:215.TT - File #2 MAIN_PRGRM - 294

Rung #296



281

Rung #297



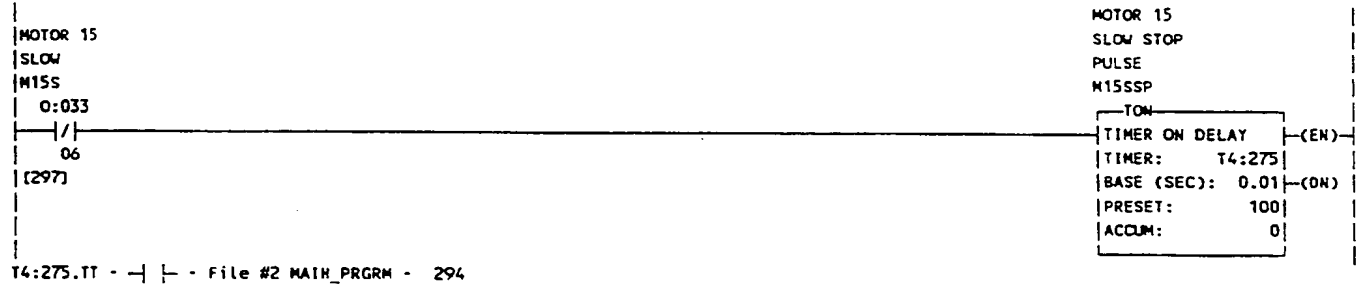
0:033/06 - | - File #2 MAIN_PRGRM - 299,300,306

-|/ - File #2 MAIN_PRGRM - 298

-() - File #2 MAIN_PRGRM - 297

T4:255.TT - | - File #2 MAIN_PRGRM - 294

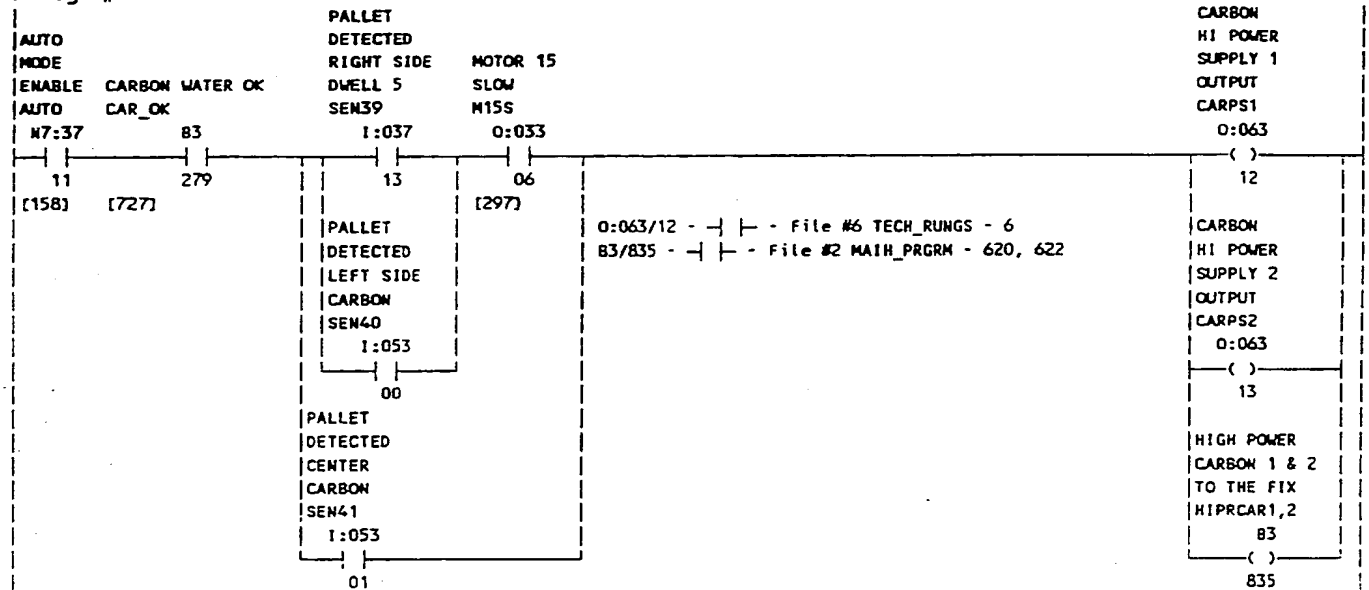
Rung #298



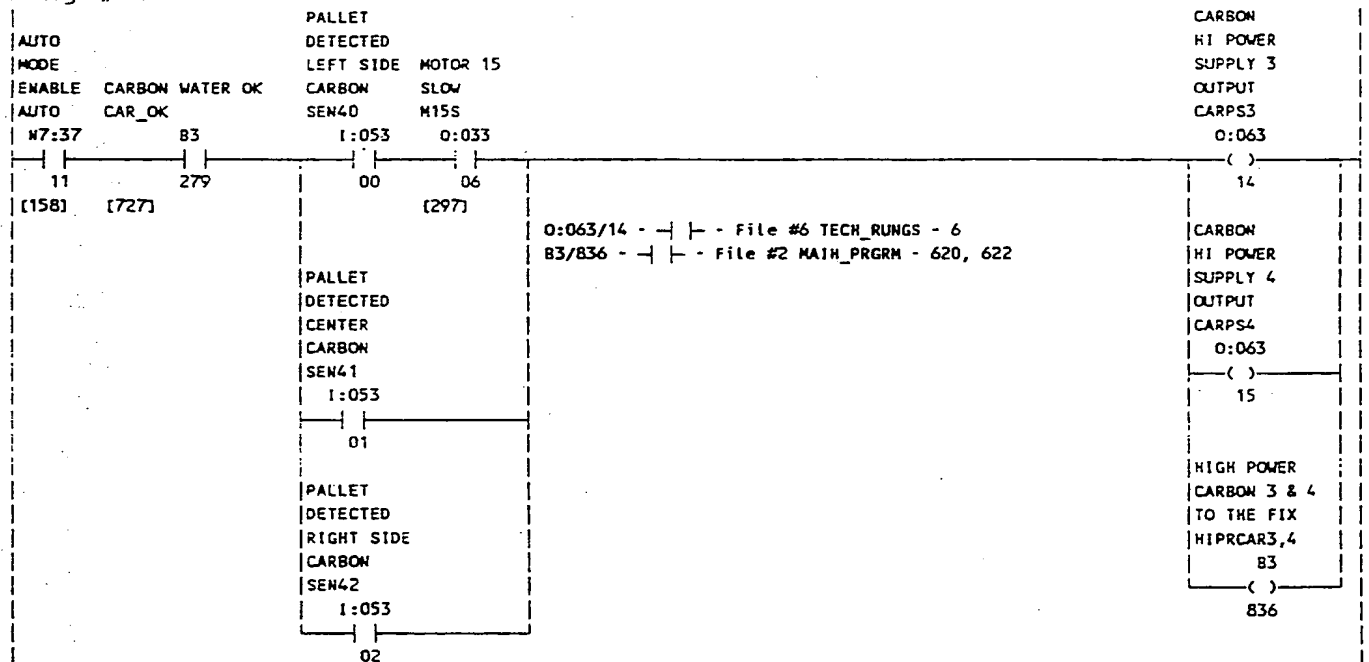
T4:275.TT - | - File #2 MAIN_PRGRM - 294

282

Rung #299



Rung #300



Rung #301



283

06 10
 T4:73 - RTO - File #2 MAIN_PRGRM - 303
 RES - File #2 MAIN_PRGRM - 301

Rung #302

PALLET PALLET PALLET
 DETECTED DETECTED DETECTED
 LEFT SIDE CENTER RIGHT SIDE
 DWELL 5 DWELL 5 DWELL 5
 SEN37 SEN38 SEN39
 1:037 1:037 1:037

CARBON TRANSIT
 CAR_TRAN
 83
 (L)
 92

83/92 - | | - File #2 MAIN_PRGRM - 303
 -(L)- - File #2 MAIN_PRGRM - 302
 -(U)- - File #2 MAIN_PRGRM - 304

Rung #303

CARBON TRANSIT
 CAR_TRAN
 83
 92

CARBON TIMER
 CAR_TMR
 RTO
 RETENTIVE TIMER ON (EN)
 TIMER: T4:73
 BASE (SEC): 1.0 (DN)
 PRESET: 1000
 ACCUM: 6

[302]

T4:73 - RTO - File #2 MAIN_PRGRM - 303
 RES - File #2 MAIN_PRGRM - 301

Rung #304

PALLET PALLET PALLET
 DETECTED DETECTED DETECTED
 LEFT SIDE CENTER RIGHT SIDE
 DWELL 6 DWELL 6 DWELL 6
 SEN43 SEN44 SEN45
 1:053 1:053 1:053

CARBON TRANSIT
 CAR_TRAN
 83
 (U)
 92

83/92 - | | - File #2 MAIN_PRGRM - 303
 -(L)- - File #2 MAIN_PRGRM - 302
 -(U)- - File #2 MAIN_PRGRM - 304

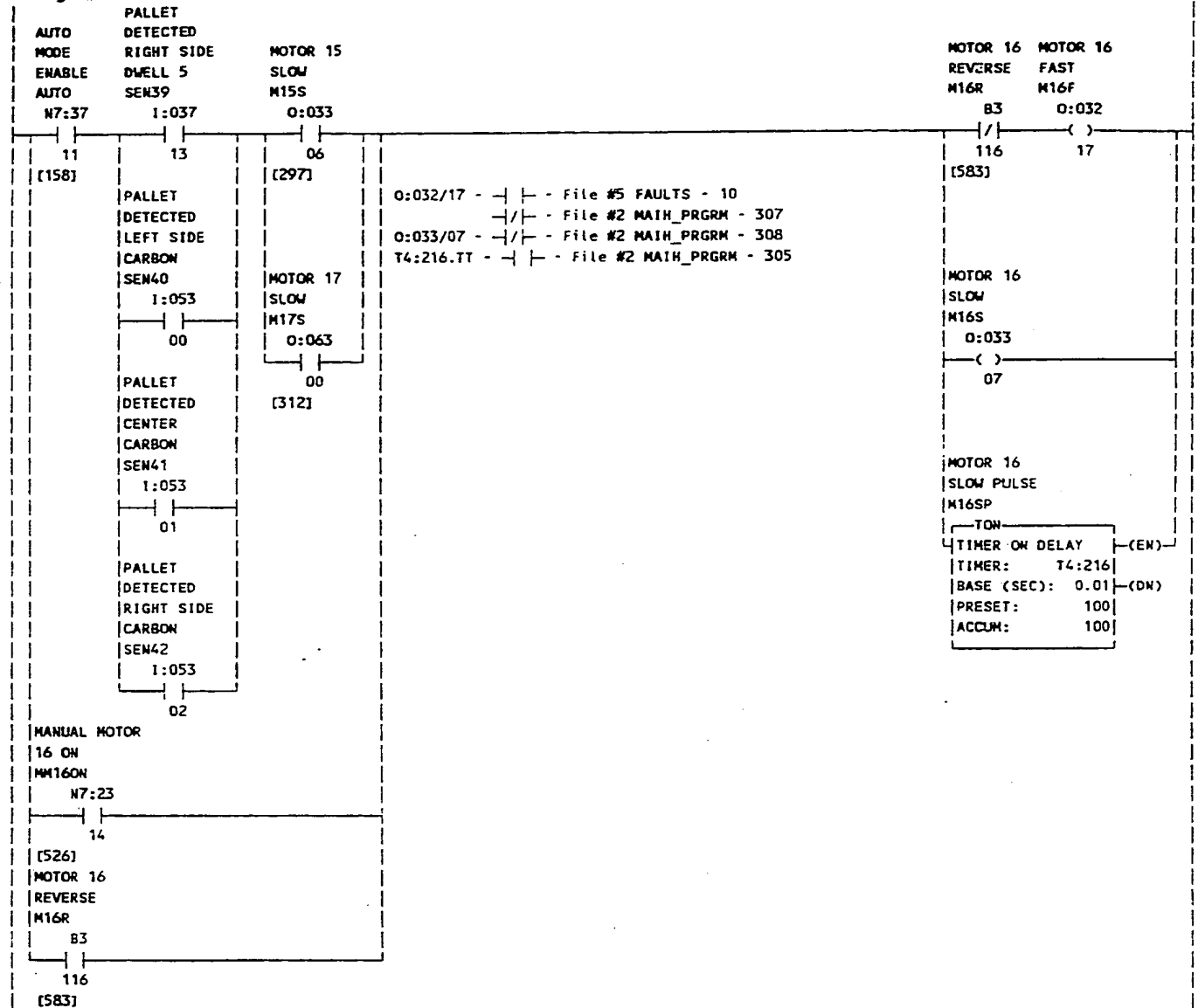
Rung #305

MOTOR DRIVE
 PULSER
 M16SP MDP
 T4:216 83
 TT 299
 [306] [14]
 M16FSP
 T4:236
 TT
 [307]
 M16SSP
 T4:276
 TT
 [308]

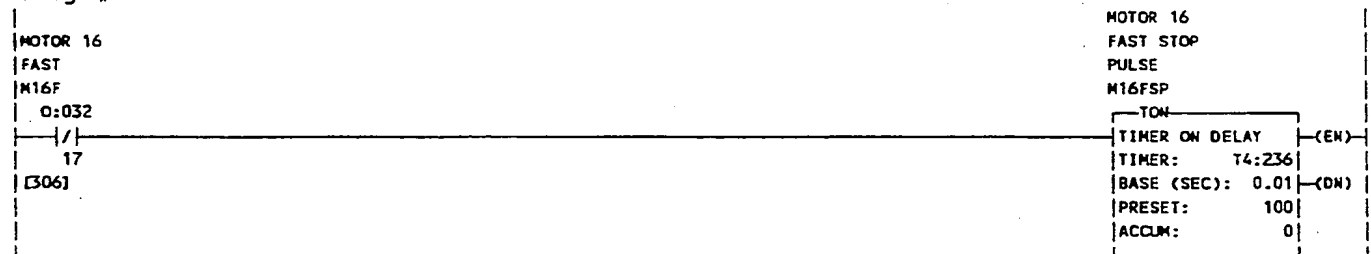
MOTOR 16
 INTERRUPT
 M16I
 0:032
 ()
 07

284

Rung #306



Rung #307



285

T4:236.TT - | | - File #2 MAIN_PRGR. 305
Rung #308

MOTOR 16
SLOW
M16S

O:033

07

[306]

MOTOR 16
SLOW STOP
PULSE
M16SSP

TON	
TIMER ON DELAY	(EN)
TIMER: T4:276	
BASE (SEC): 0.01	(DN)
PRESET: 100	
ACCUM: 0	

T4:276.TT - | | - File #2 MAIN_PRGR - 305
Rung #309

MOTOR DRIVE
PULSER
M17FP MDP

T4:217

83

TT

[310]

M17FSP

T4:237

TT

[311]

M17SP

T4:257

TT

[312]

M17SSP

T4:277

TT

[313]

MOTOR 17
INTERRUPT
M17I

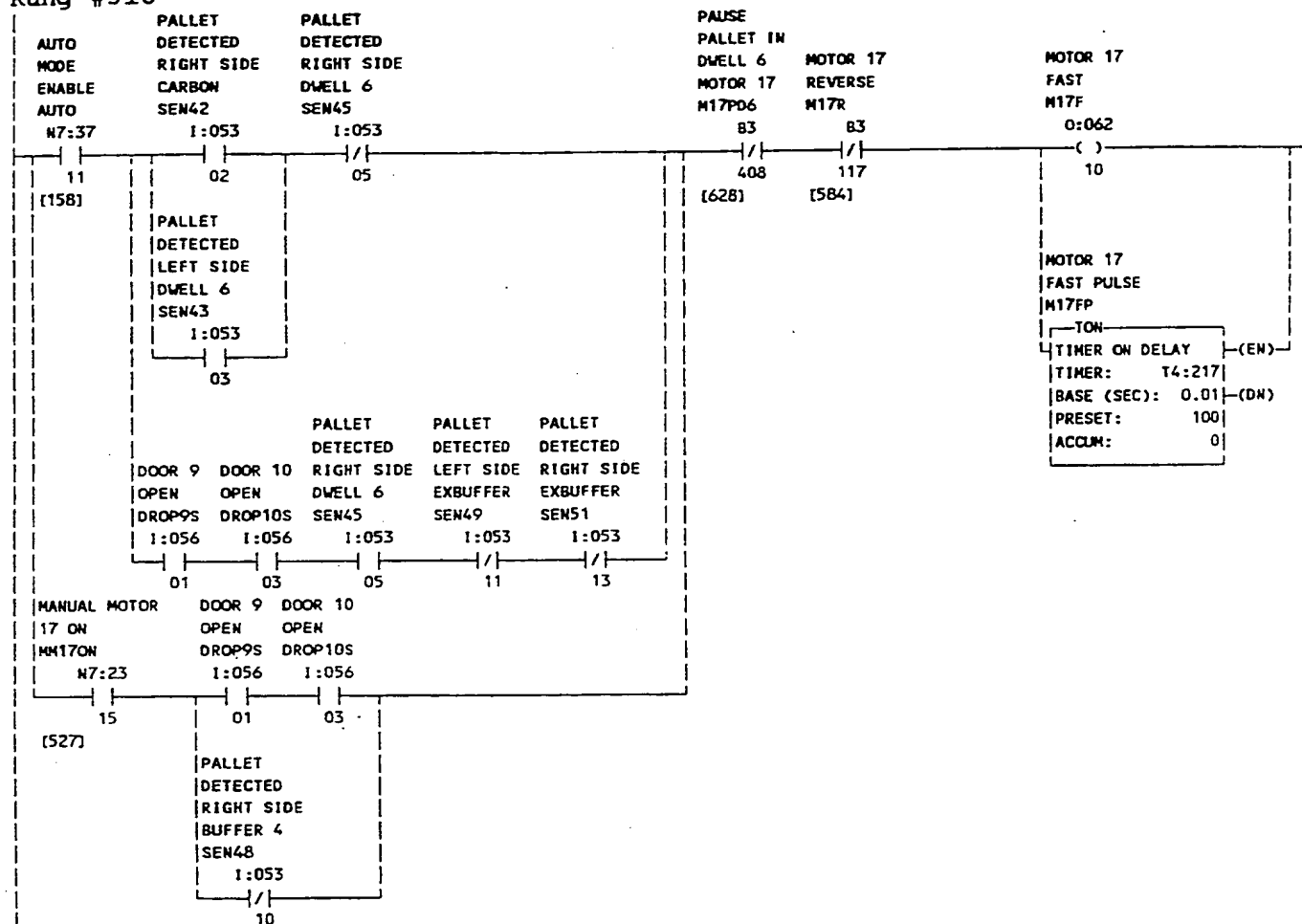
O:062

()

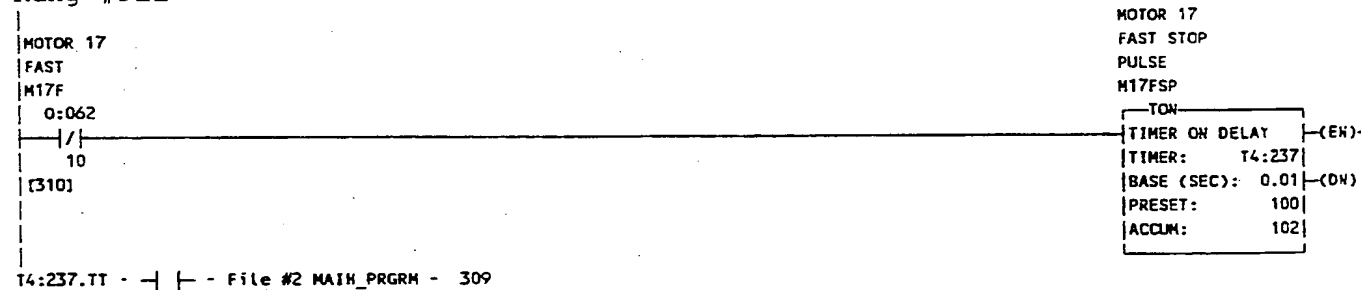
00

286

Rung #310



0:062/10 - | | - File #5 FAULTS - 11
 - | | - File #2 MAIN_PRGRM - 311
 - () - File #2 MAIN_PRGRM - 310
 T4:217.TT - | | - File #2 MAIN_PRGRM - 309
 Rung #311



T4:237.TT - | | - File #2 MAIN_PRGRM - 309

Rung #321

MOTOR 19
FAST
M19F
O:062

12
[320]

MOTOR 19
FAST STOP
PULSE
M19FSP

TON
TIMER ON DELAY (EN)
TIMER: T4:239
BASE (SEC): 0.01 (DN)
PRESET: 100
ACCUM: 0

T4:239.TT - - File #2 MAIN_PRGRM - 319

Rung #322

MANUAL MOTOR
19 ON
M19ON
N7:24

DOOR 11
OPEN
DROP11S
I:056

PAUSE
PALLET IN
EXITBUFFER
MOTOR 19
M19PXB
B3

MOTOR 19
SLOW
M19S
O:063

1
[529]

05
[628]

409
[628]

()
02

PALLET
DETECTED
RIGHT SIDE
EXBUFFER
SEN51
I:053
13

O:063/02 - - File #2 MAIN_PRGRM - 323
T4:259.TT - - File #2 MAIN_PRGRM - 319

MOTOR 19
SLOW PULSE
M19SP

TON
TIMER ON DELAY (EN)
TIMER: T4:259
BASE (SEC): 0.01 (DN)
PRESET: 100
ACCUM: 0

MOTOR 19
REVERSE
M19R
B3
119
[586]

DOOR 9 DOOR 10
OPEN OPEN
DROP9S DROP10S
I:056 I:056
01 03

PALLET
DETECTED
LEFT SIDE
EXBUFFER
SEN49
I:053
11

Rung #323

MOTOR 19
SLOW
M19S
O:063

02
[322]

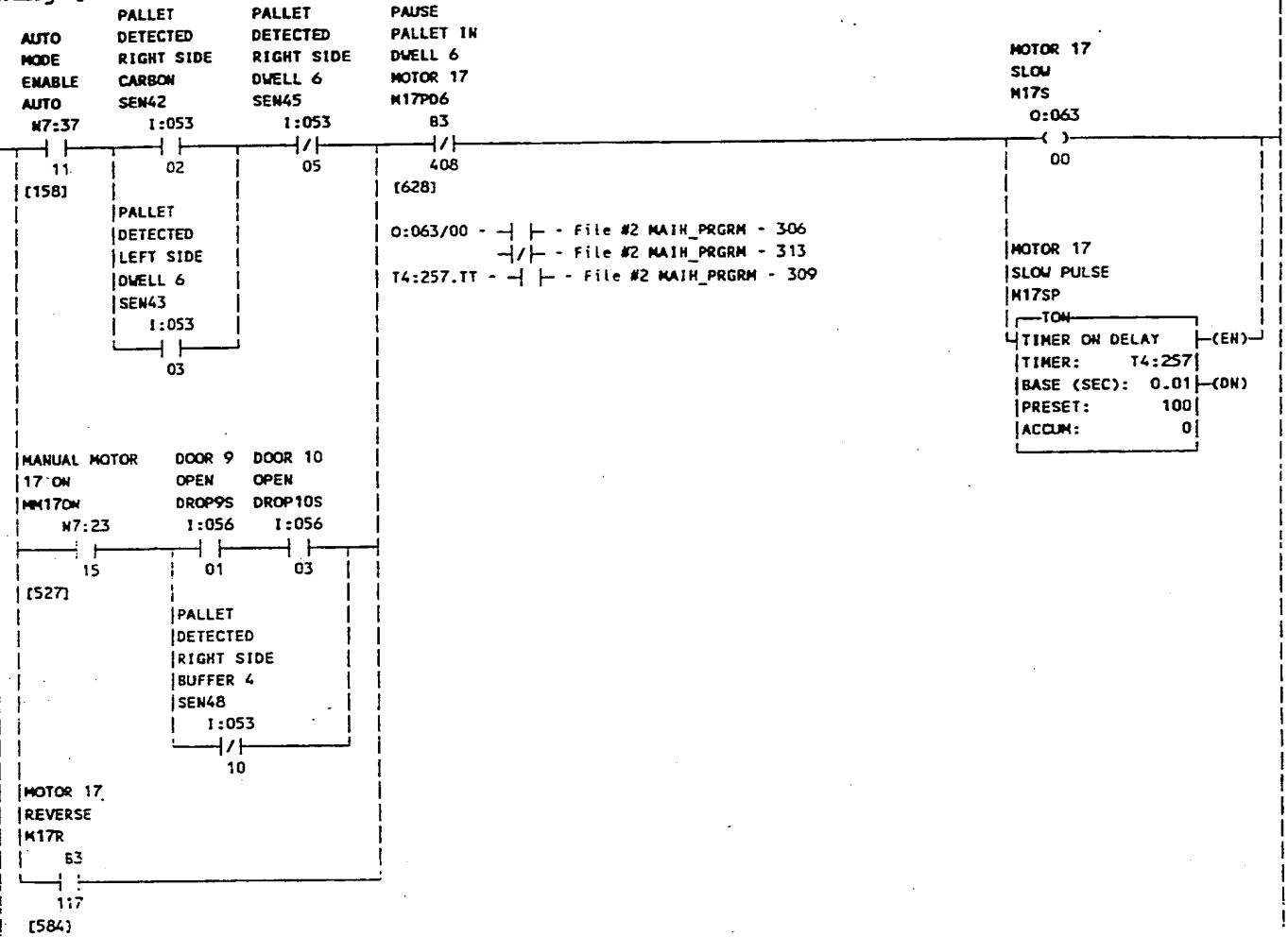
MOTOR 19
SLOW STOP
PULSE
M19SSP

TON
TIMER ON DELAY (EN)
TIMER: T4:279
BASE (SEC): 0.01 (DN)
PRESET: 100
ACCUM: 101

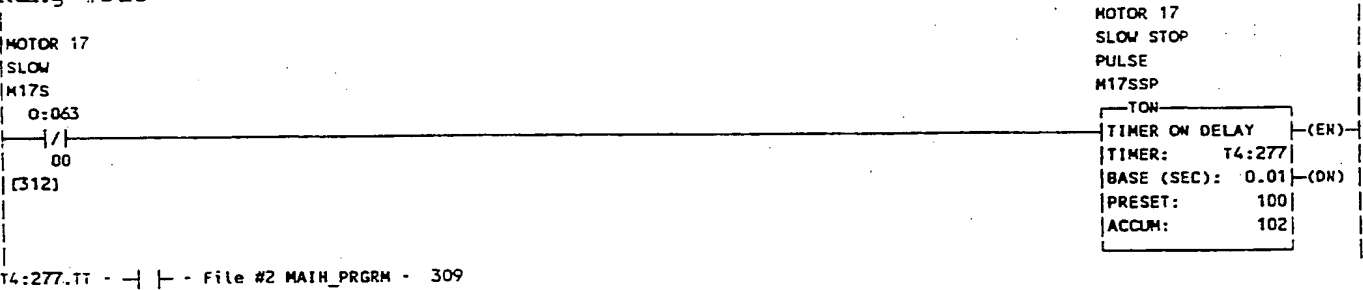
T4:279.TT - - File #2 MAIN_PRGRM - 319

288

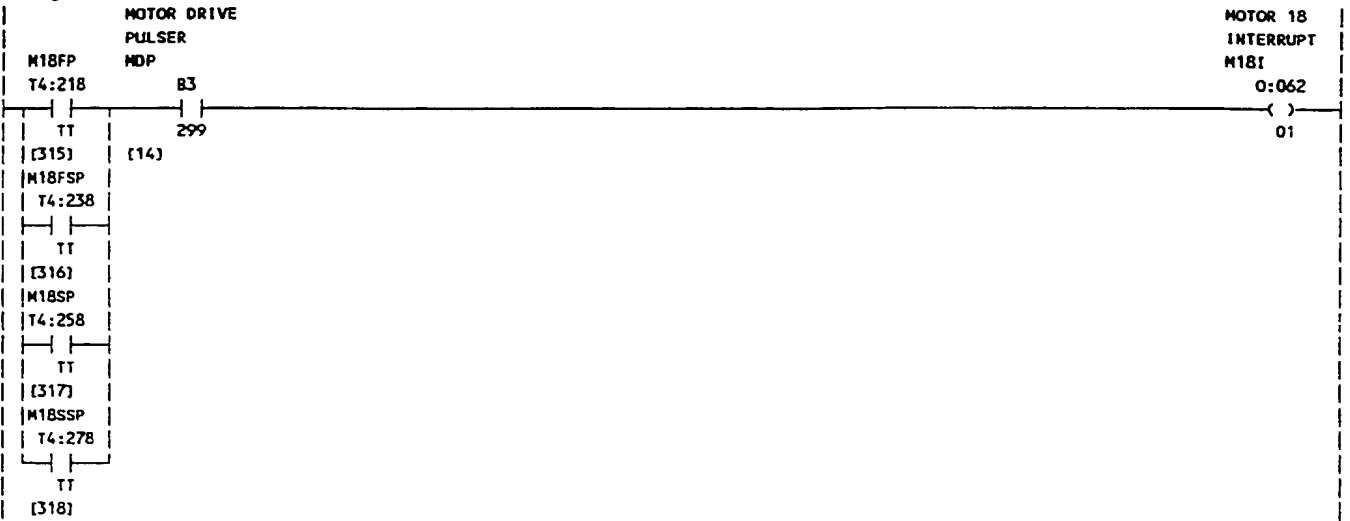
Rung #312



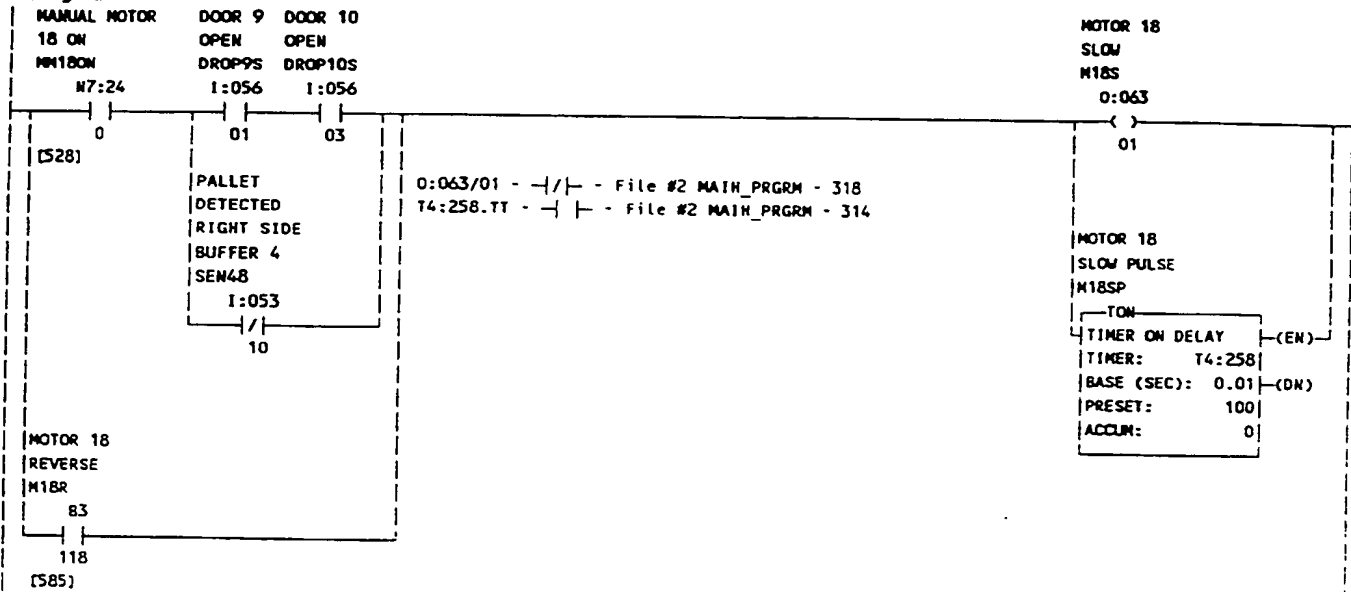
Rung #313



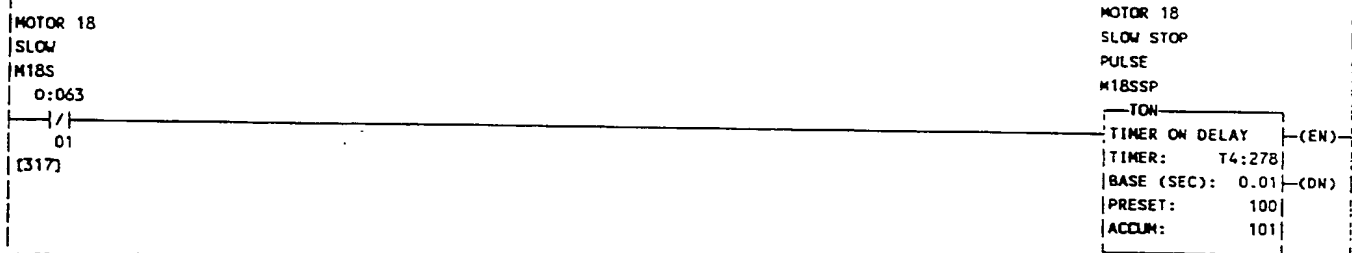
Rung #314



Rung #317

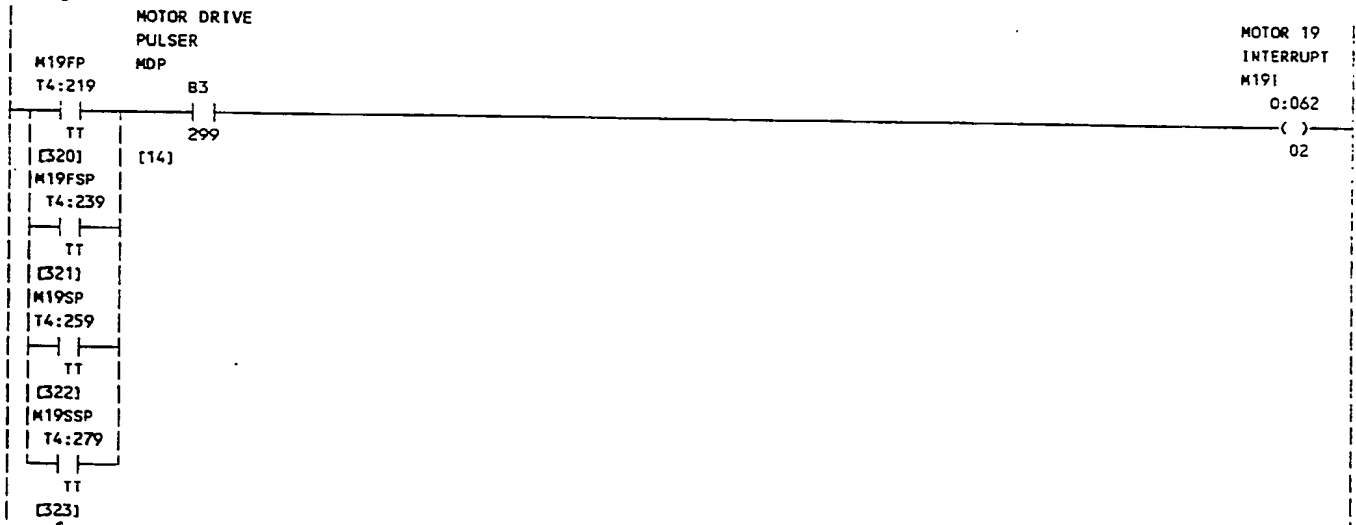


Rung #318

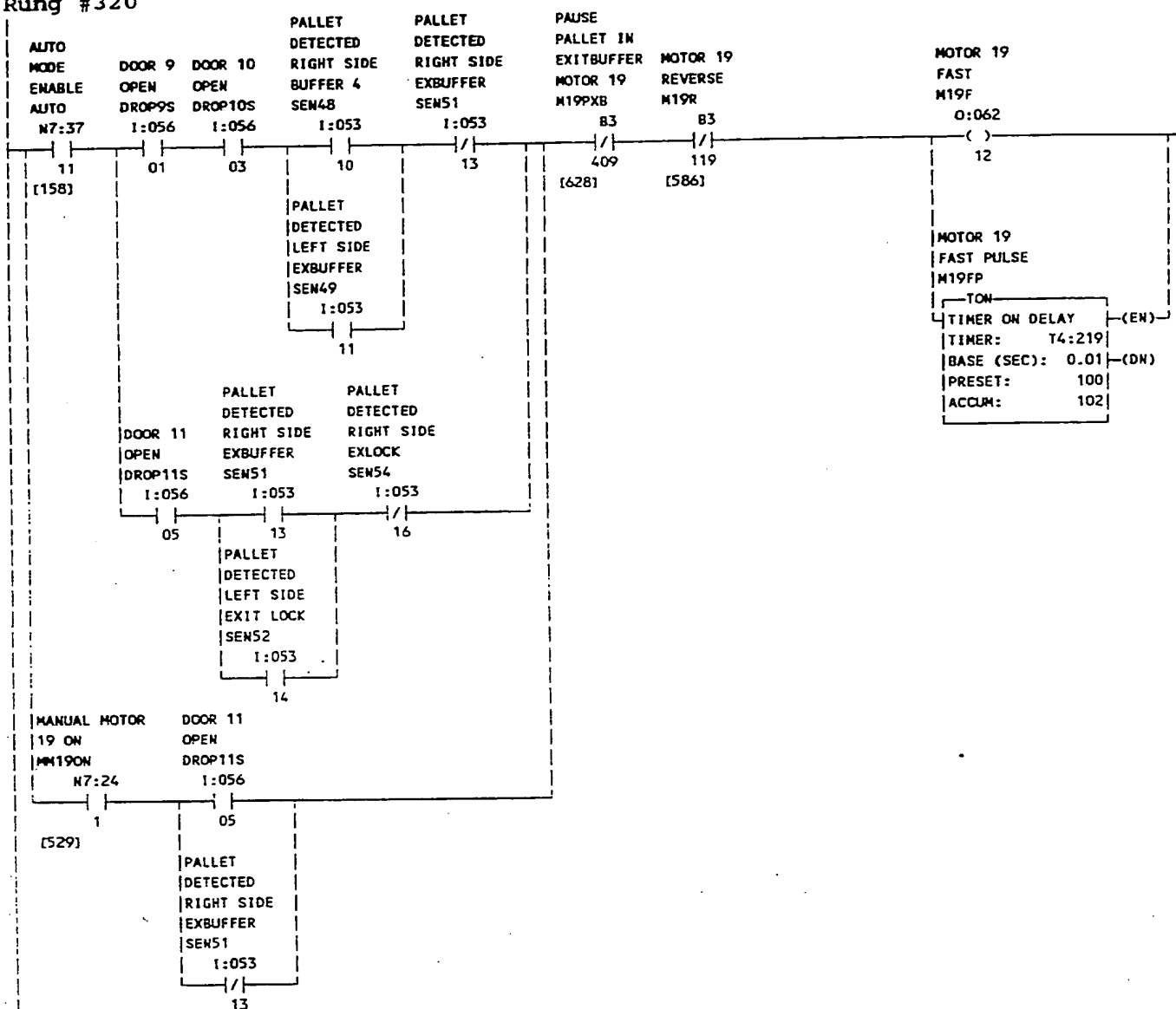


T4:278.TT - /| - File #2 MAIN_PRGRM - 314

Rung #319



Rung #320



O:062/12 - | | - File #5 FAULTS - 12
 -|/| - File #2 MATH_PRGRM - 321
 -() - File #2 MATH_PRGRM - 320
 T4:219.TT - | | - File #2 MATH_PRGRM - 319

293

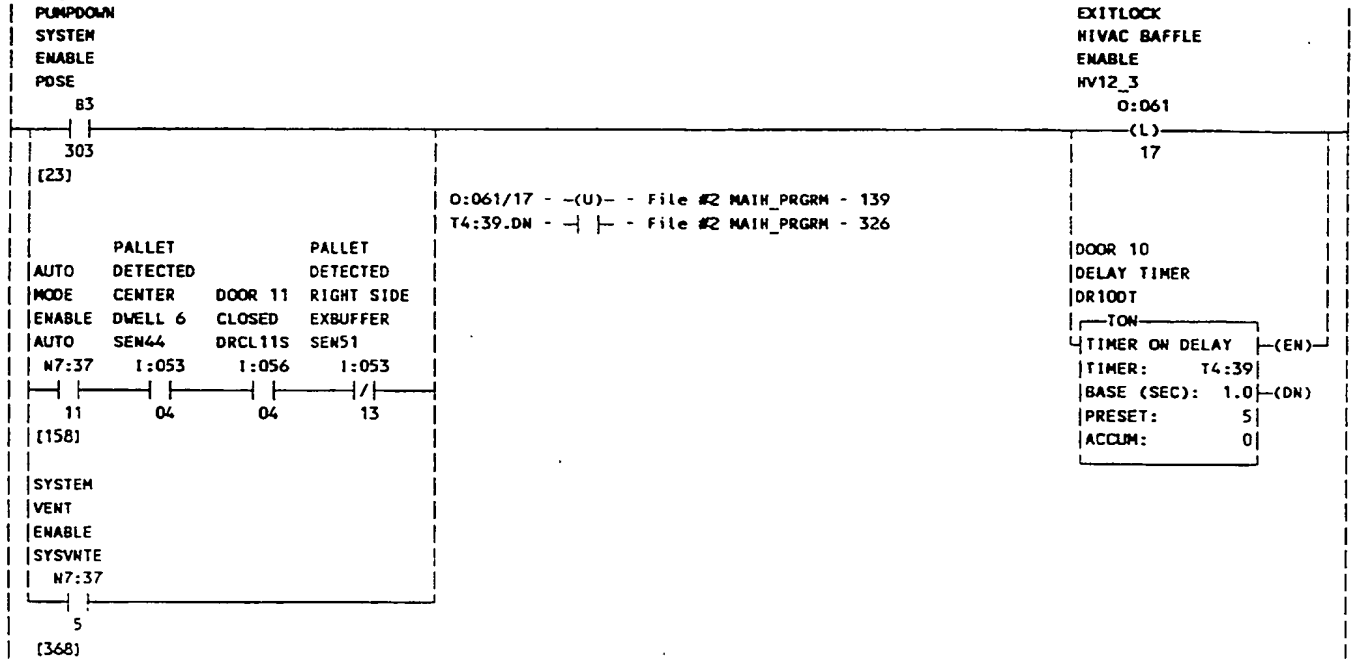
WO 92/17621

294

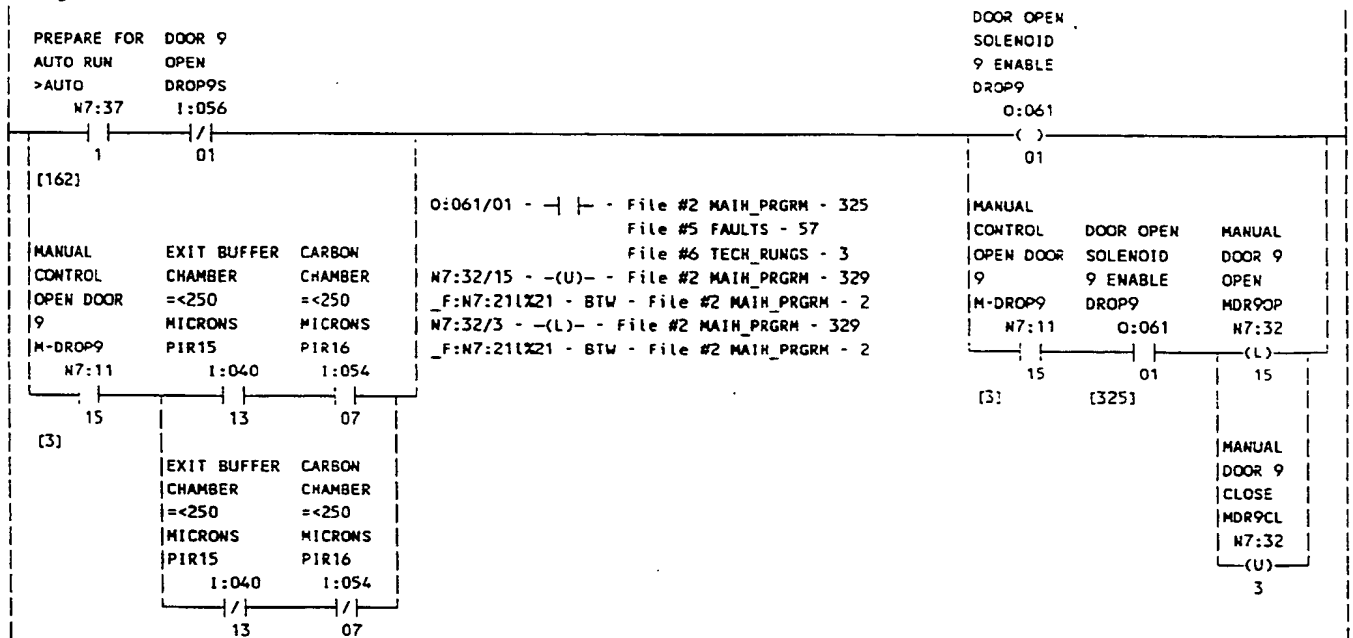
PCT/US92/00722

295

Rung #324

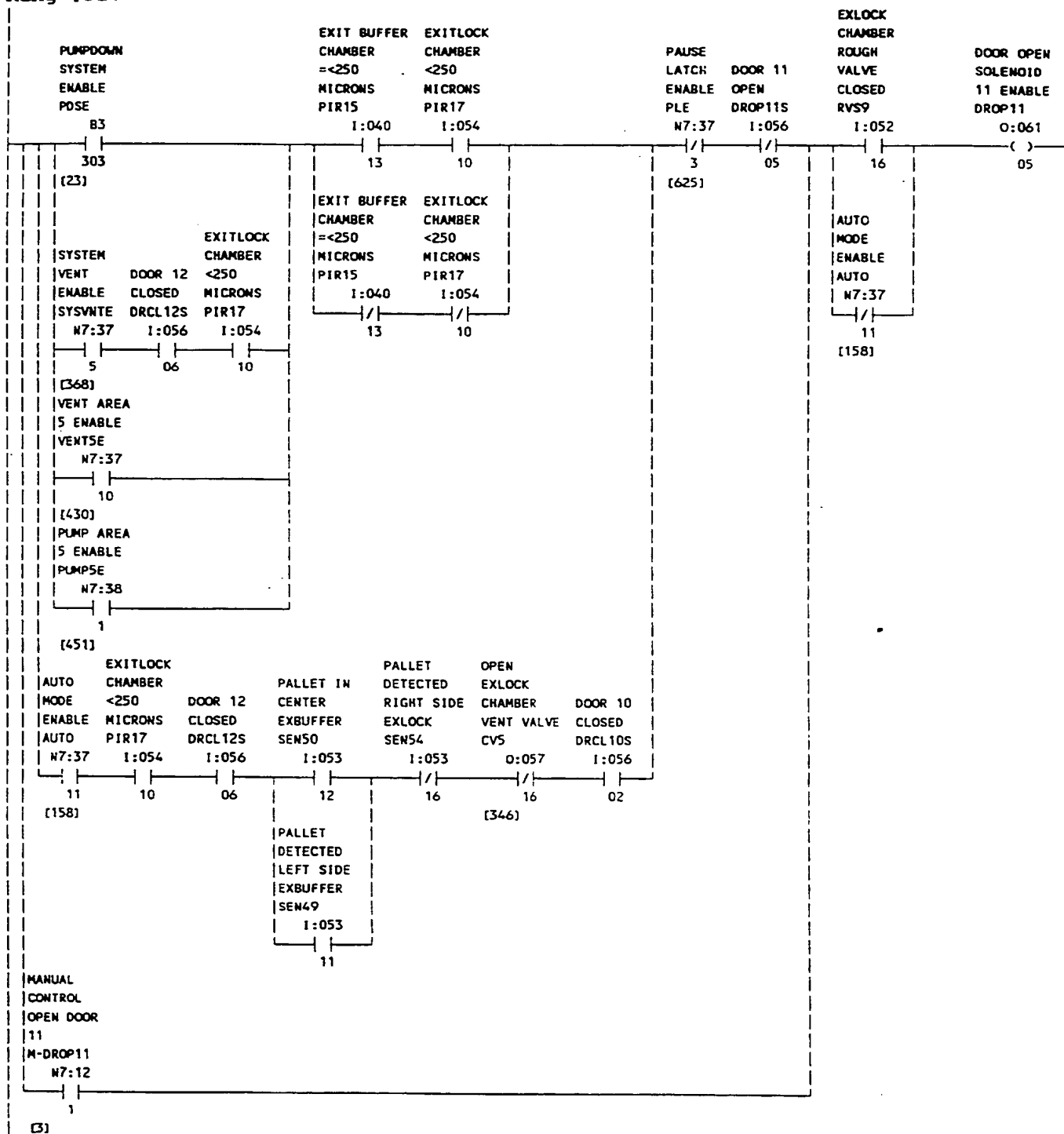


Rung #325



297

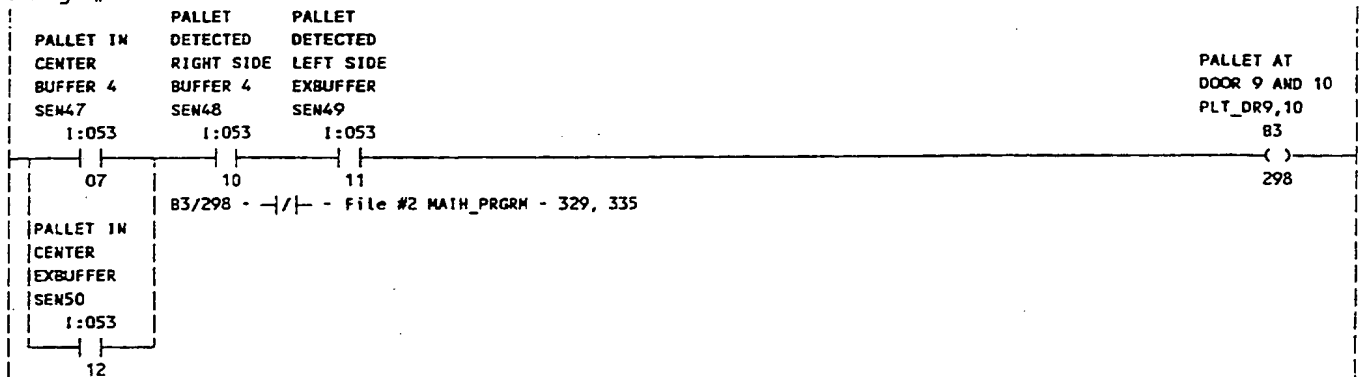
F:\N7:211\21 - BTW - File #2 MAIN_PRG. 2
Rung #327



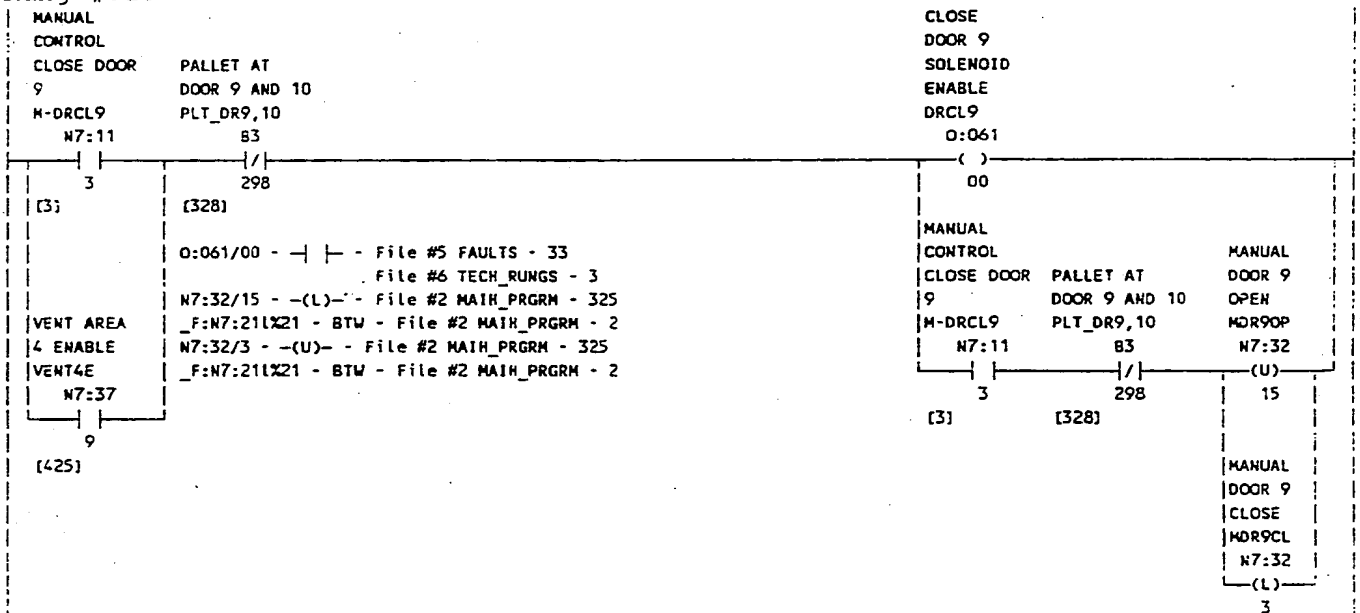
298

0:061/05 - | | - File #5 FAULTS - 1
 File #6 TECH_RUNGS - 3
 - () - File #2 MAIN_PRGRM - 327

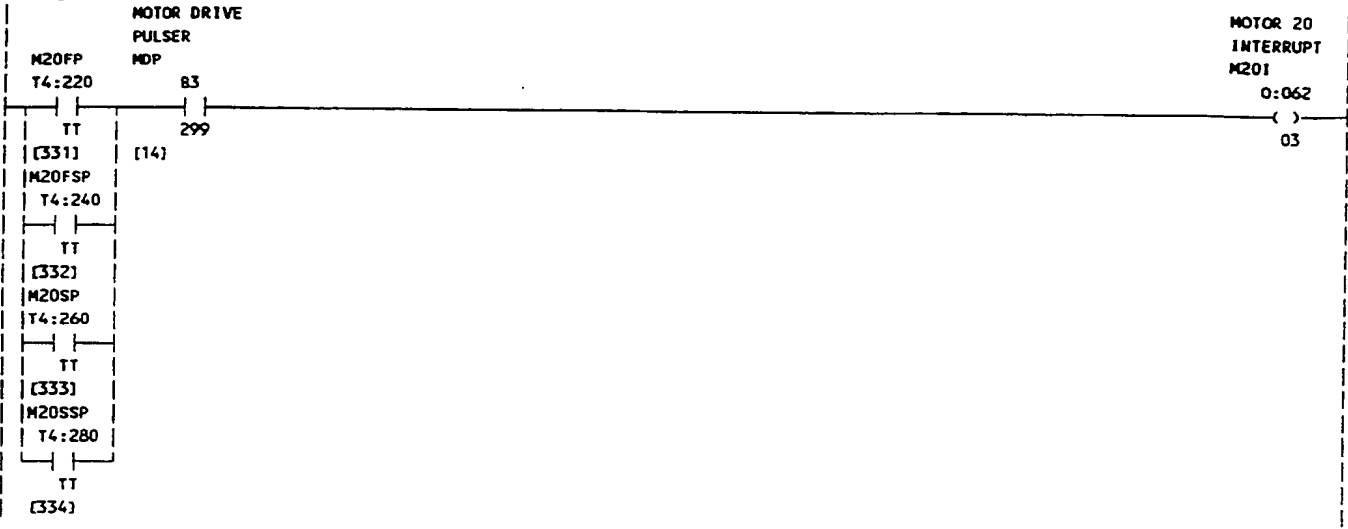
Rung #328



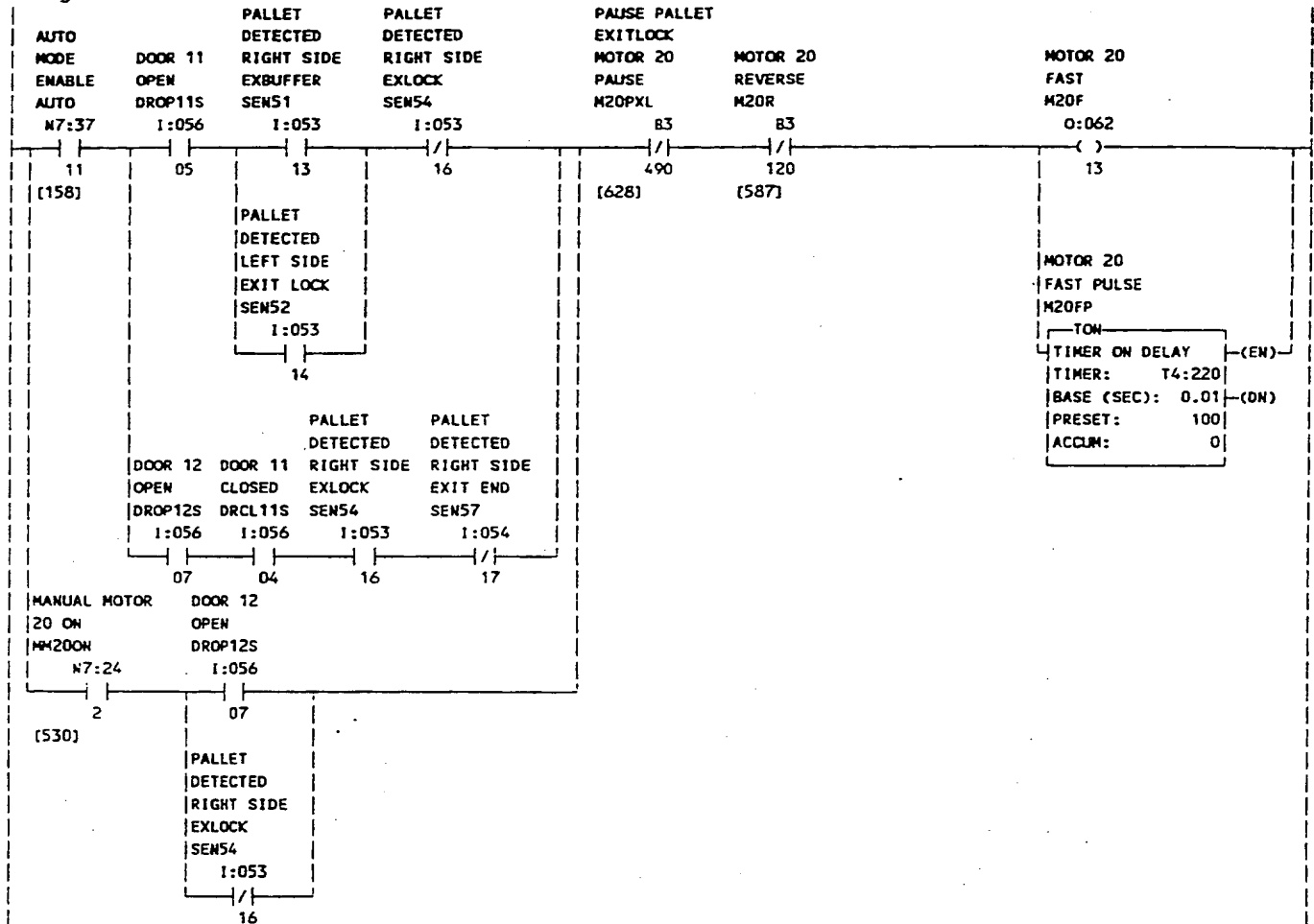
Rung #329



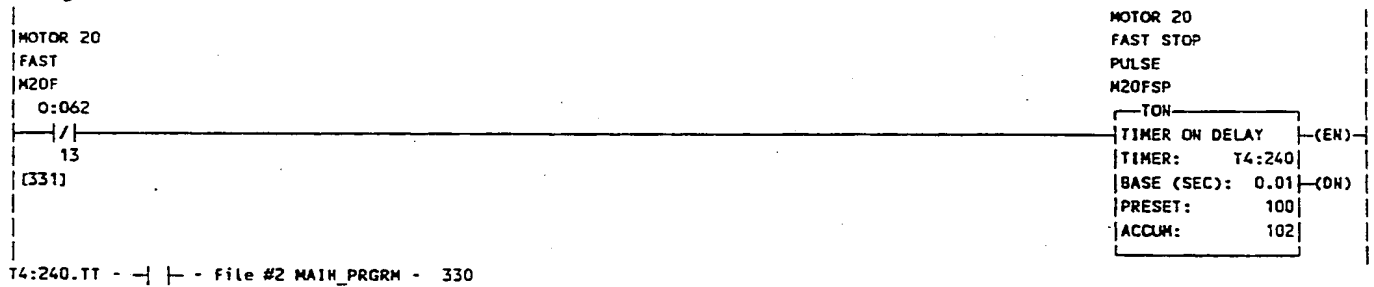
Rung #330



Rung #331

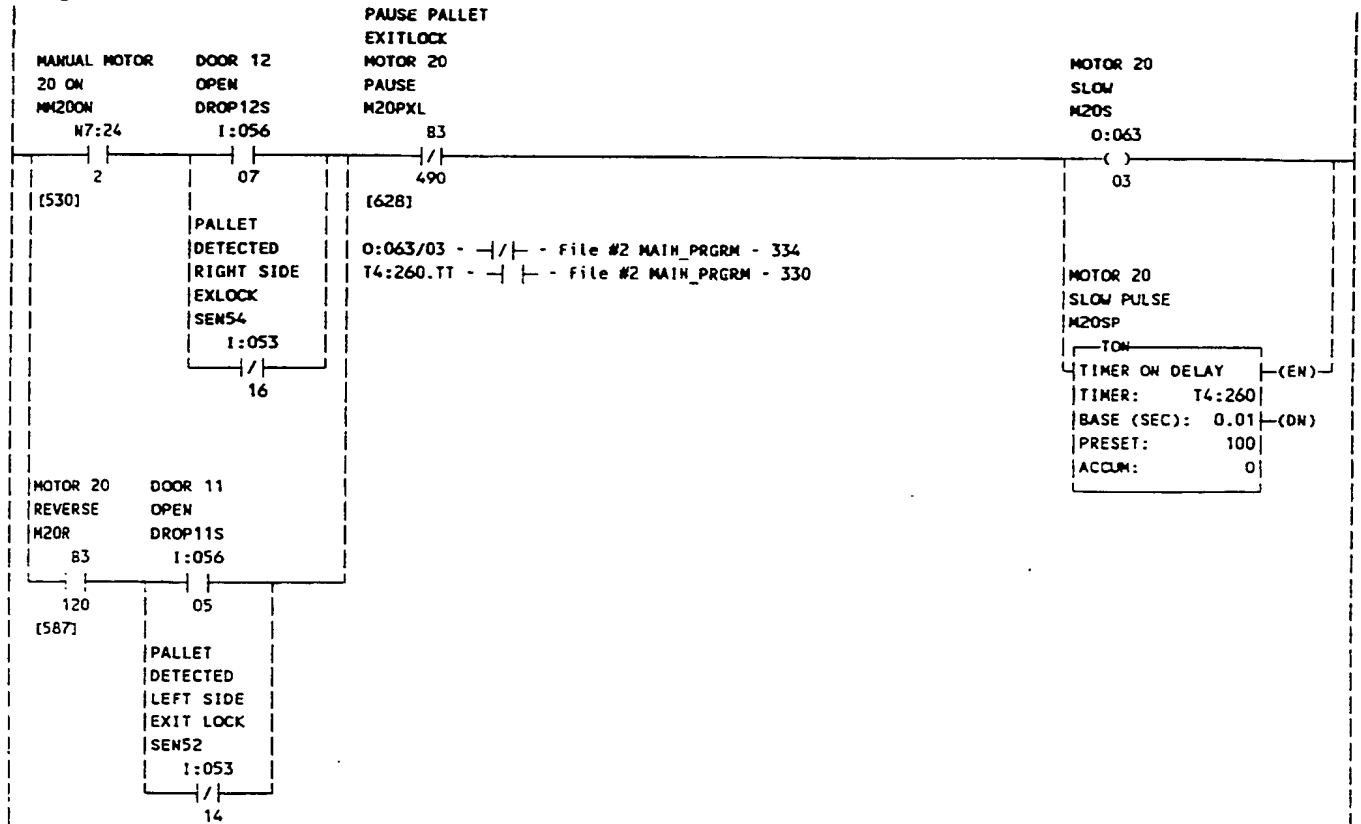


Rung #332

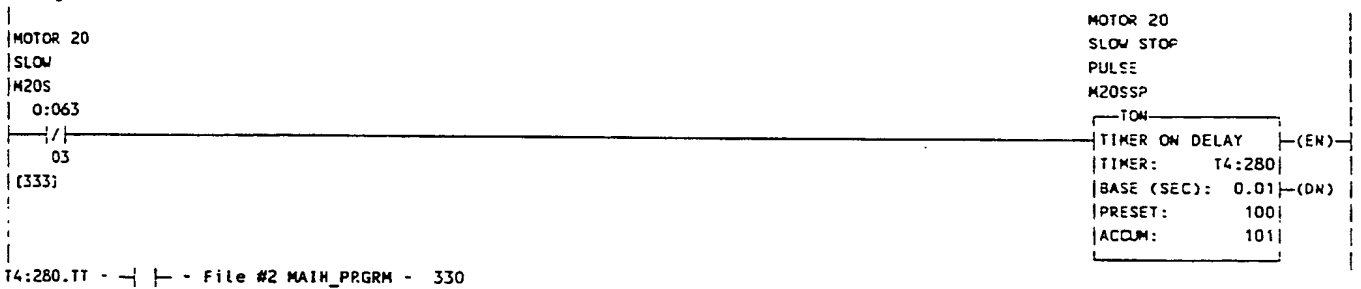


321

Rung #333

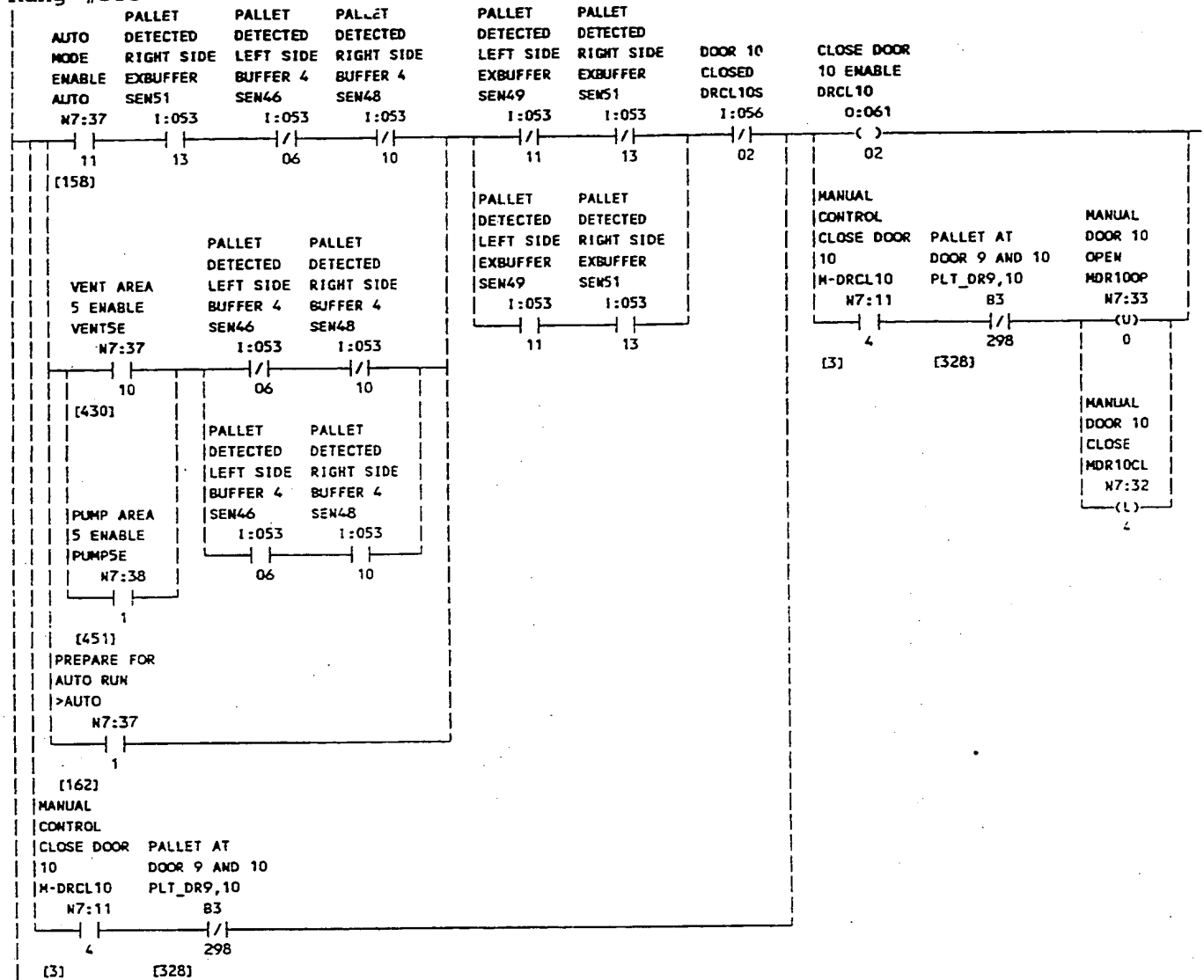


Rung #334



302

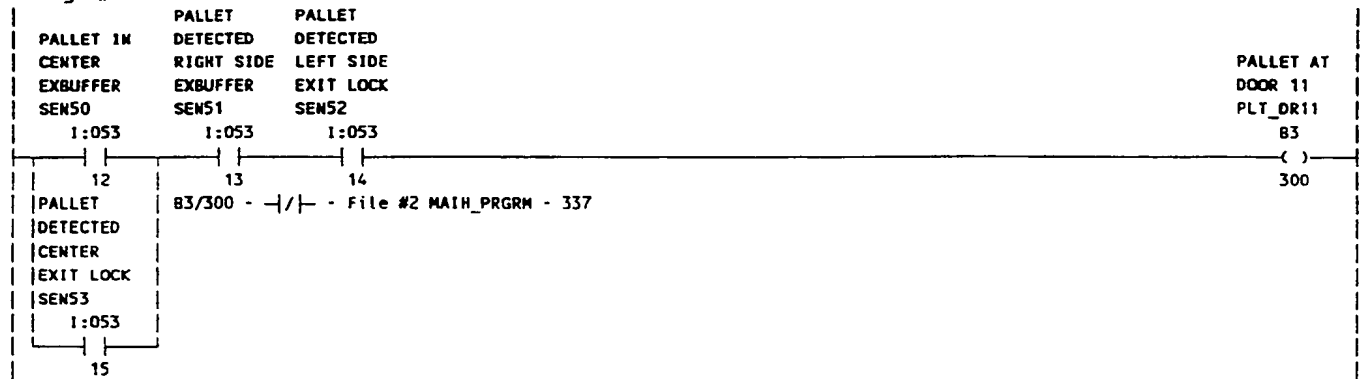
Rung #335



[3] [328]
 0:061/02 - | - File #5 FAULTS - 35
 File #6 TECH_RUNGS - 3
 -() - File #2 MAIN_PRGRM - 335
 N7:33/0 - -(L)- File #2 MAIN_PRGRM - 326
 -(U)- File #2 MAIN_PRGRM - 335
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:32/4 - -(L)- File #2 MAIN_PRGRM - 335
 -(U)- File #2 MAIN_PRGRM - 326
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

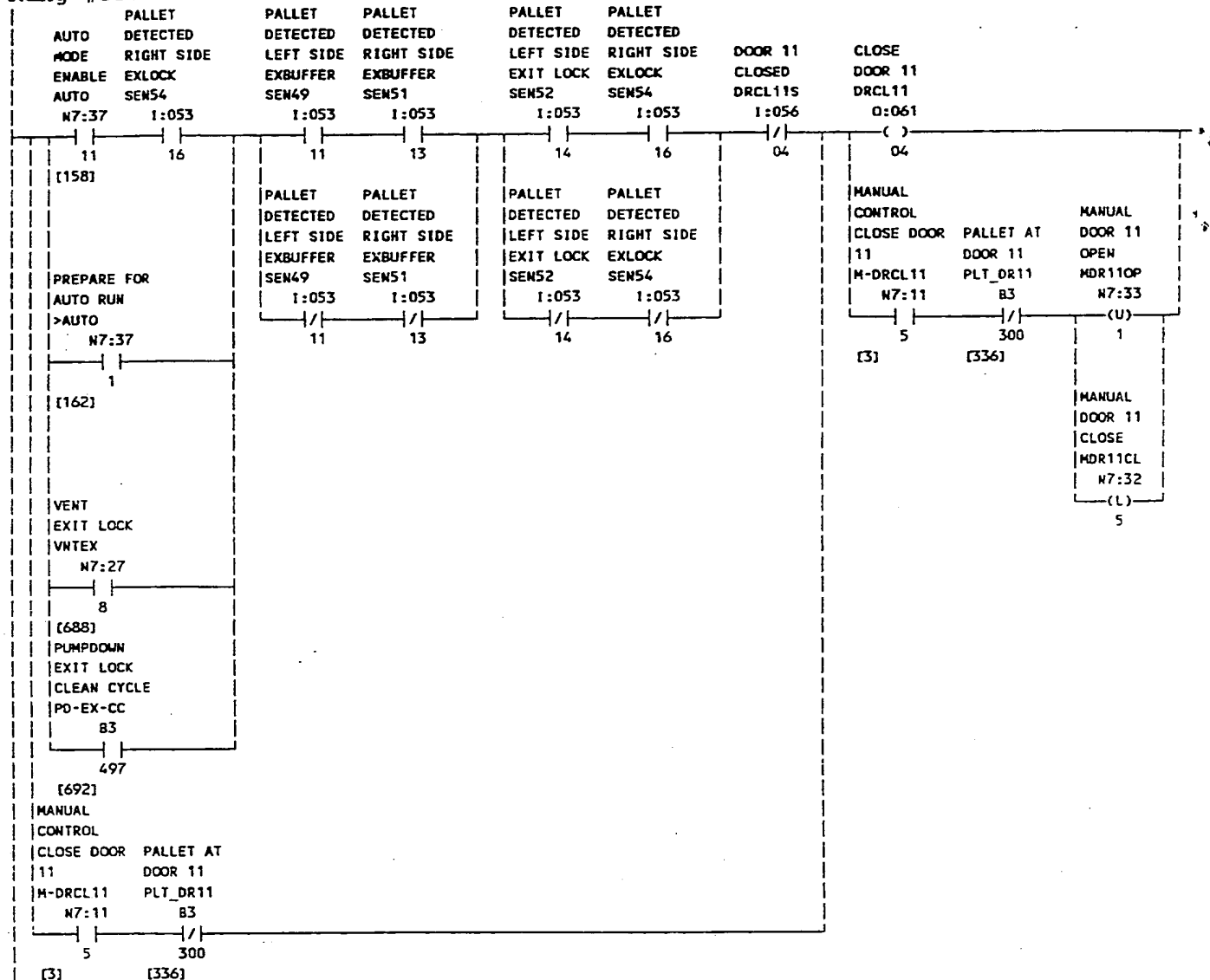
303

Rung #336



304

Rung #337



O:061/04 - | - File #5 FAULTS - 37

File #6 TECH_RUNGS - 3

-() - File #2 MAIN_PRGRM - 337

_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #338

AUTOPULSE
T4:282

TT

[158]

COMPUTER
SIGNAL FOR
AUTO MODE
ENABLE OK
AUTO COMPAUTO
N7:37 N7:16

11

11

[158] [3]

Rung #339

VENT-PUMP
CYCLE EXIT
LOCK
VNT-PD-EX
N7:27

9

[690]

VENT
EXIT LOCK
VNTEX
N7:27

8

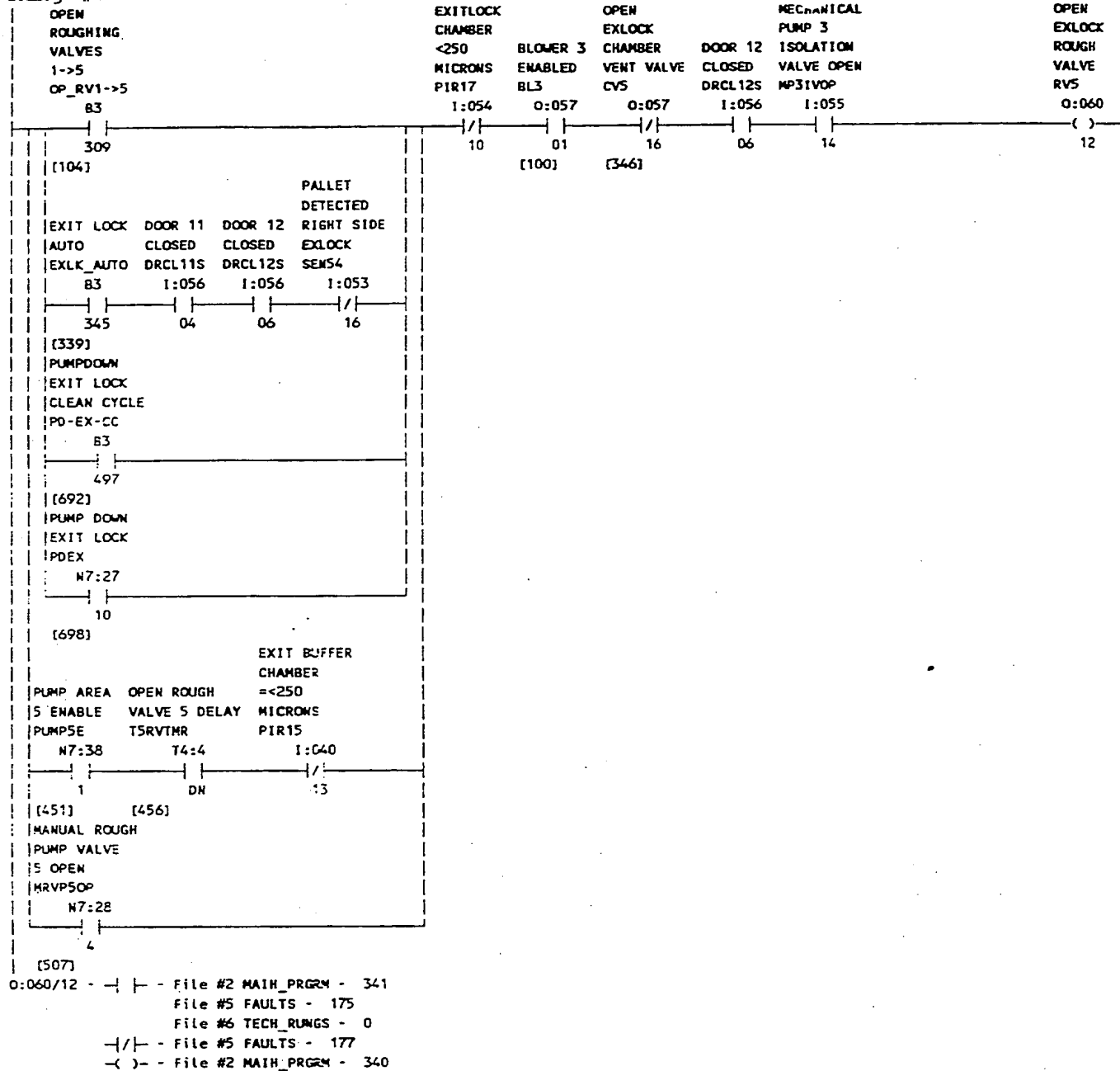
[688]
AUTO MODE
DISABLE
TS10
N7:16

2

[3]

83/345 - | | - File #2 MAIN_PRGRM - 340, 353
-(U)- - File #2 MAIN_PRGRM - 33983/345 - | | - File #2 MAIN_PRGRM - 340, 353
-(L)- - File #2 MAIN_PRGRM - 338EXIT LOCK
AUTO
EXLK_AUTO
83
(L)
345EXIT LOCK
AUTO
EXLK_AUTO
83
(U)
345

Rung #340



Rung #341

```
|      OPEN
|AUTO  EXLOCK
|MODE  ROUGH
|ENABLE VALVE
|AUTO  RV5
|N7:37 0:060
```

A number line with points labeled 11 and 12. Below the line, the intervals are labeled [158] and [340].

EXIT LOCK
ROUGHING
TIMER
EXRUFFTMR

TON		
TIMER ON DELAY		(EW)
TIMER:	14:166	
BASE (SEC):	1.0	(DW)
PRESET:	60	
ACCUM:	0	

T4:166.DW - | | - File #2 MAIN_PRGRM - 342

Rung #342

EXRUFFTMR
T4:166

```
EXIT LOCK
ROUGHING
>60 SEC
EXLKRUFF>60S
```

83

- (L) -

[341]

B3/817 - J | - File #2 MAIH_PRGRM - 626
 -(L)- - File #2 MAIH_PRGRM - 342
 -(U)- - File #2 MAIH_PRGRM - 343

Rung = 343

PAUSE
DISABLE
TS12
N7:16

```
EXIT LOCK
ROUGHING
>60 SEC
EXLKRUFF>60S
```

83

-(U)-

{ 3 }

B3/817 - 1 1 - File #2 MAIN_PRGRM - 626
 - (L) - File #2 MAIN_PRGRM - 342
 - (U) - File #2 MAIN_PRGRM - 343

Rung $\equiv 344$

VENT 5
STAGE 1
VSST 1
B3

420
[432]

VENT 5 STAGE1
VENT 5 DELAY
TIMER
VSCVSDYTHR

```

TON
TIMER ON DELAY (EN)
TIMER:      T4:30
BASE (SEC): 1.0 (DN)
PRESET:      5
ACCUM:       0

```

T4:30.DM - - File #2 MAIN_PRGRM - 346

Rung #345

DOOR 11
CLOSED
DRCL11S
1:056

 $\frac{1}{2}$

VENT OPEN
DELAY ON
DOOR 11
CLOSE
VDDR11CL

```

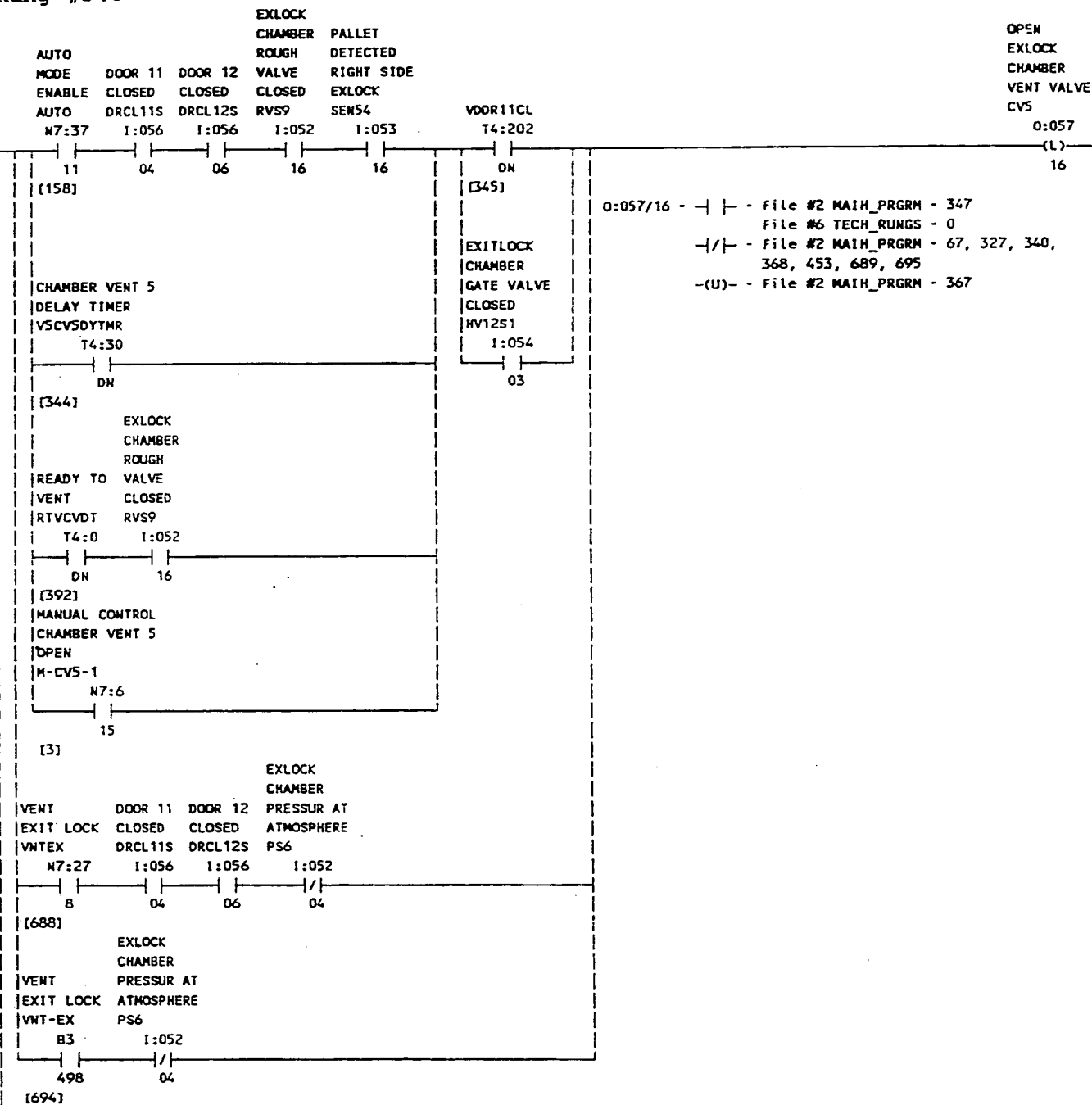
TON
TIMER ON DELAY (EN)
TIMER: 14:202
BASE (SEC): 1.0 (DN)
PRESET: 1
ACCUM: 1

```

T4:202.DM - - File #2 MAIN PRGRM - 346

308

Rung #346



309

Rung #347

AUTO OPEN
MODE EXLOCK
ENABLE CHAMBER PAUSE
ENABLE VENT VALVE DISABLE
AUTO CVS TS12

N7:37 0:057 N7:16
11 16 4
(158) (346) (3)

EXIT LOCK
VENT TIMER
EXVNTTIMER

TON
TIMER ON DELAY (EN)
TIMER: T4:99
BASE (SEC): 1.0 (DN)
PRESET: 100
ACCUM: 0

T4:99.DN - - File #2 MAIN_PRGRM - 348

Rung #348

EXVNTTIMER

T4:99

DN

(347)

B3/815 - - File #2 MAIN_PRGRM - 626

-(L) - File #2 MAIN_PRGRM - 348

-(U) - File #2 MAIN_PRGRM - 349

Rung #349

PAUSE

DISABLE

TS12

N7:16

4

(3)

B3/815 - - File #2 MAIN_PRGRM - 626

-(L) - File #2 MAIN_PRGRM - 348

-(U) - File #2 MAIN_PRGRM - 349

Rung #350

DOOR 12

OPEN

DROP12S

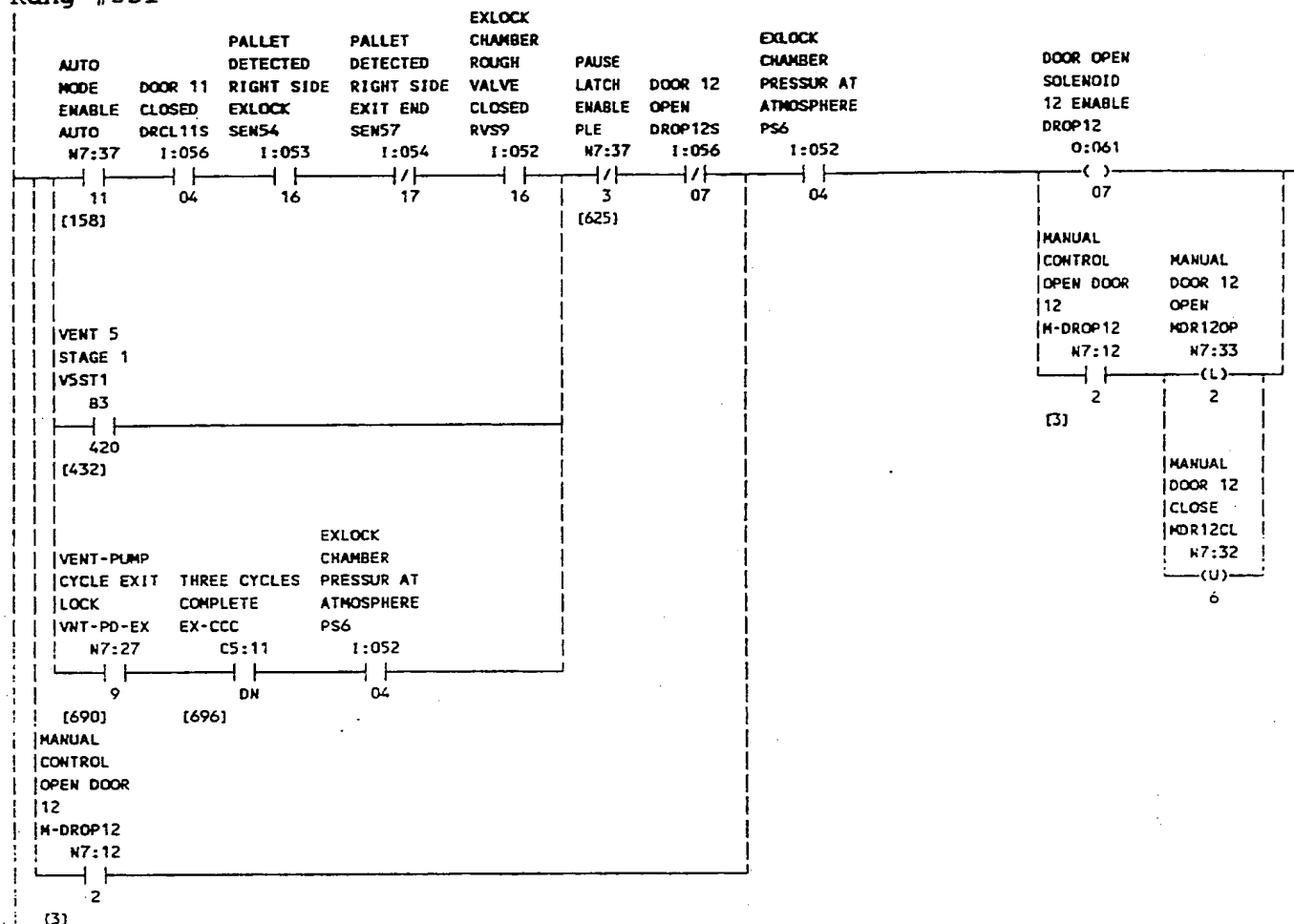
1:056

07

EXIT LOCK
VENT>30 SECS
EXLKVNT>30SECS
83
(U)
815

EXITLOCK
AIR SWEEP
SOLENOID
EXSWEEP
0:061
()
10

Rung #351



(3)

O:061/07 - | - File #5 FAULTS - 63

- () - File #2 MAIN_PRGRM - 351

N7:33/2 - -(L)- - File #2 MAIN_PRGRM - 351

-(U)- - File #2 MAIN_PRGRM - 353

_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2

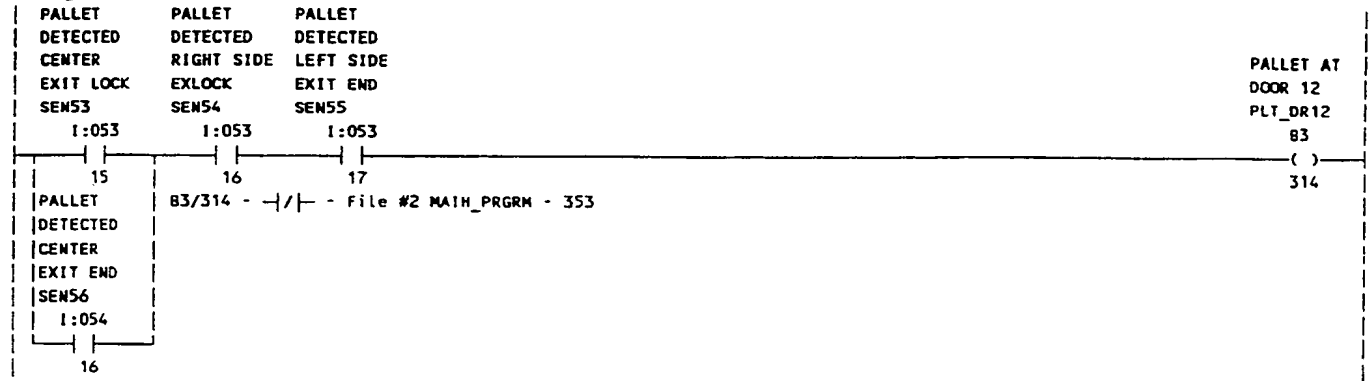
N7:32/6 - -(L)- - File #2 MAIN_PRGRM - 353

-(U)- - File #2 MAIN_PRGRM - 351

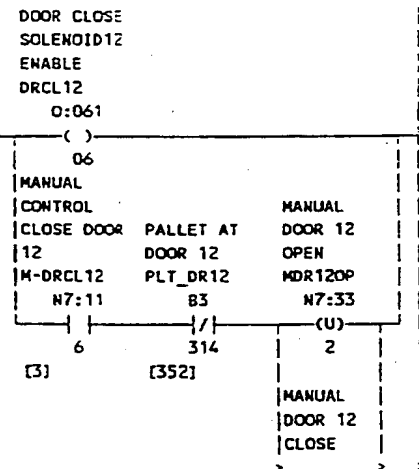
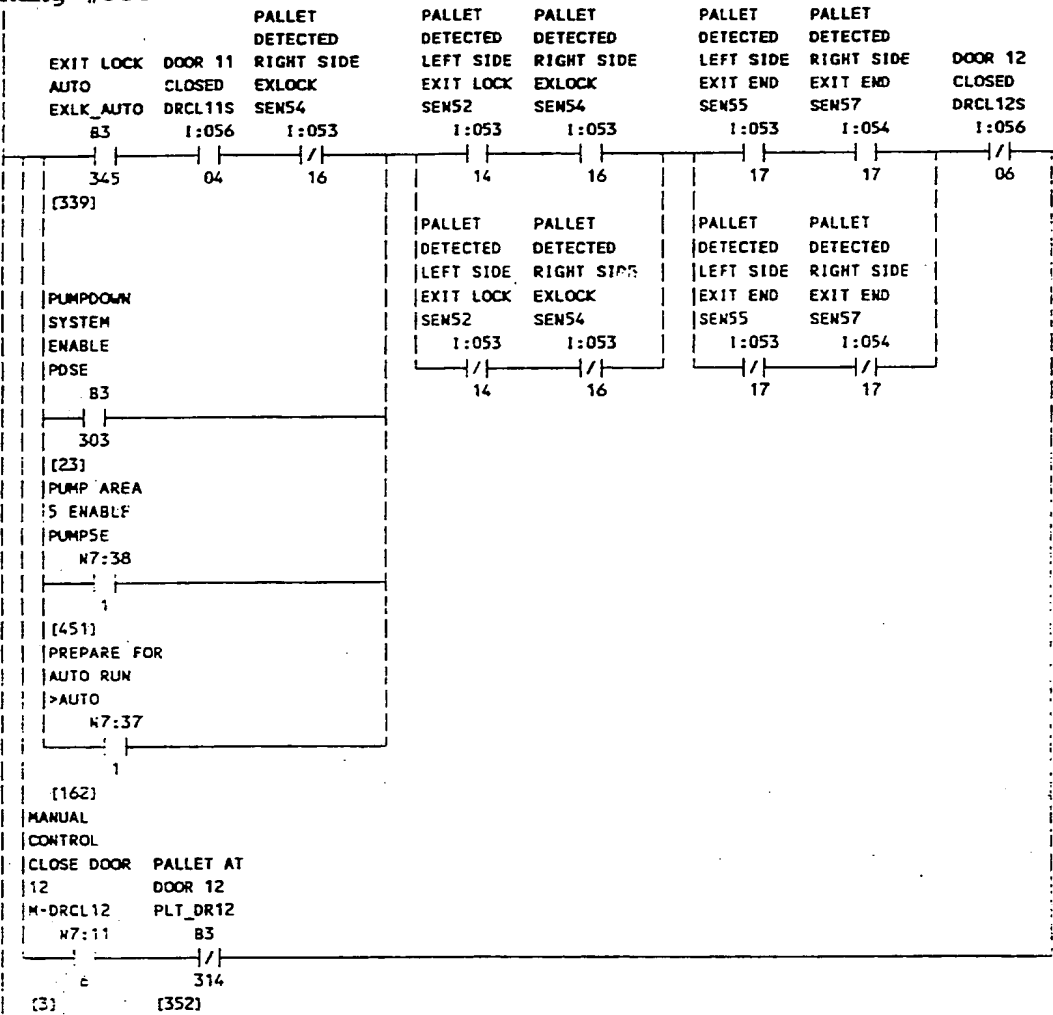
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2

311

Rung #352



Rung #353

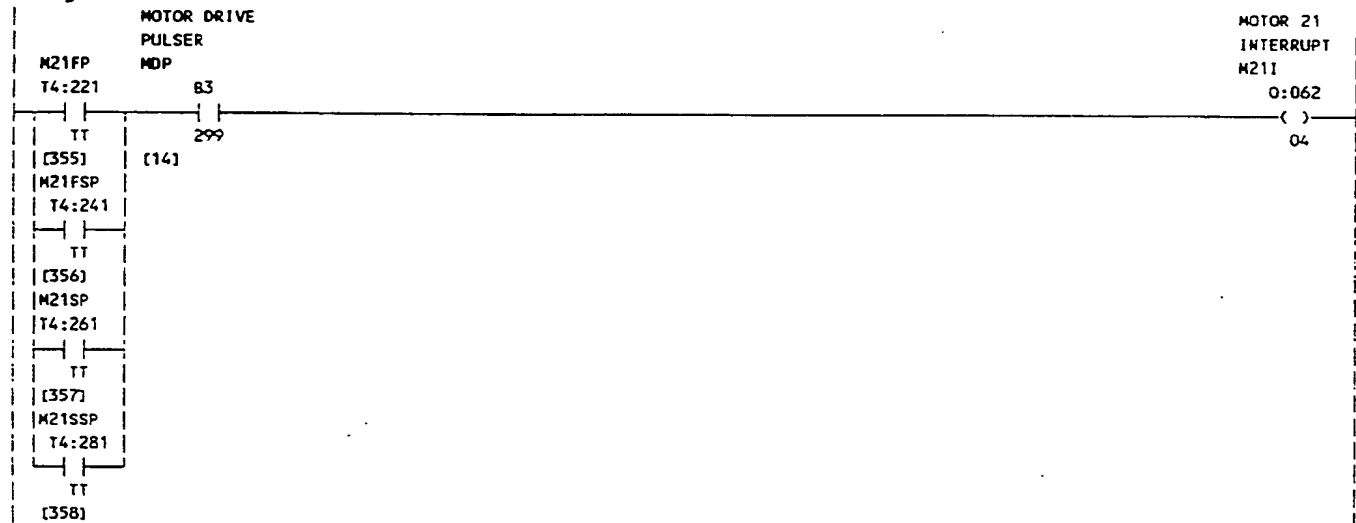


313

MDR12CL
N7:32
(L)
6

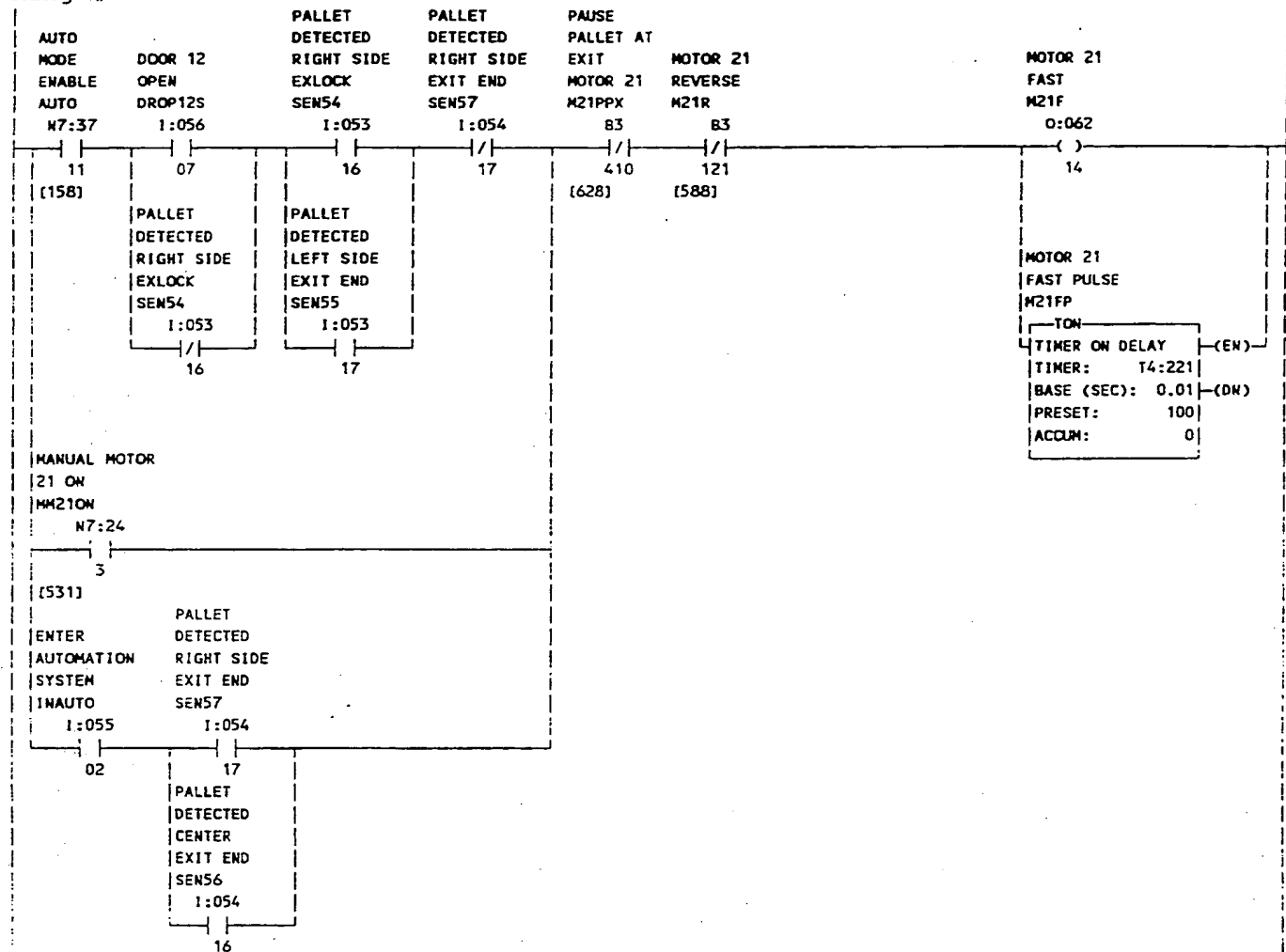
0:061/06 - | - File #5 FAULTS - 39
 File #6 TECH_RUNGS - 3
 -() - File #2 MAIN_PRGRM - 353
 N7:33/2 - -(L)- File #2 MAIN_PRGRM - 351
 -(U)- File #2 MAIN_PRGRM - 353
 F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
 N7:32/6 - -(L)- File #2 MAIN_PRGRM - 353
 -(U)- File #2 MAIN_PRGRM - 351
 F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

Rung #354

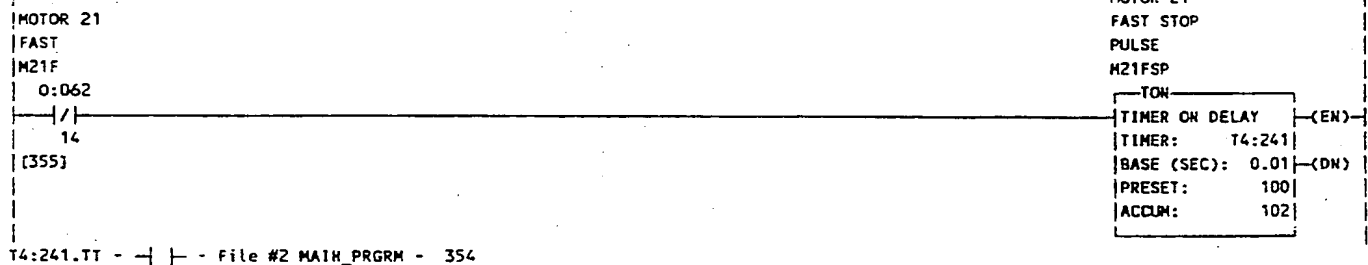


314

Rung #355



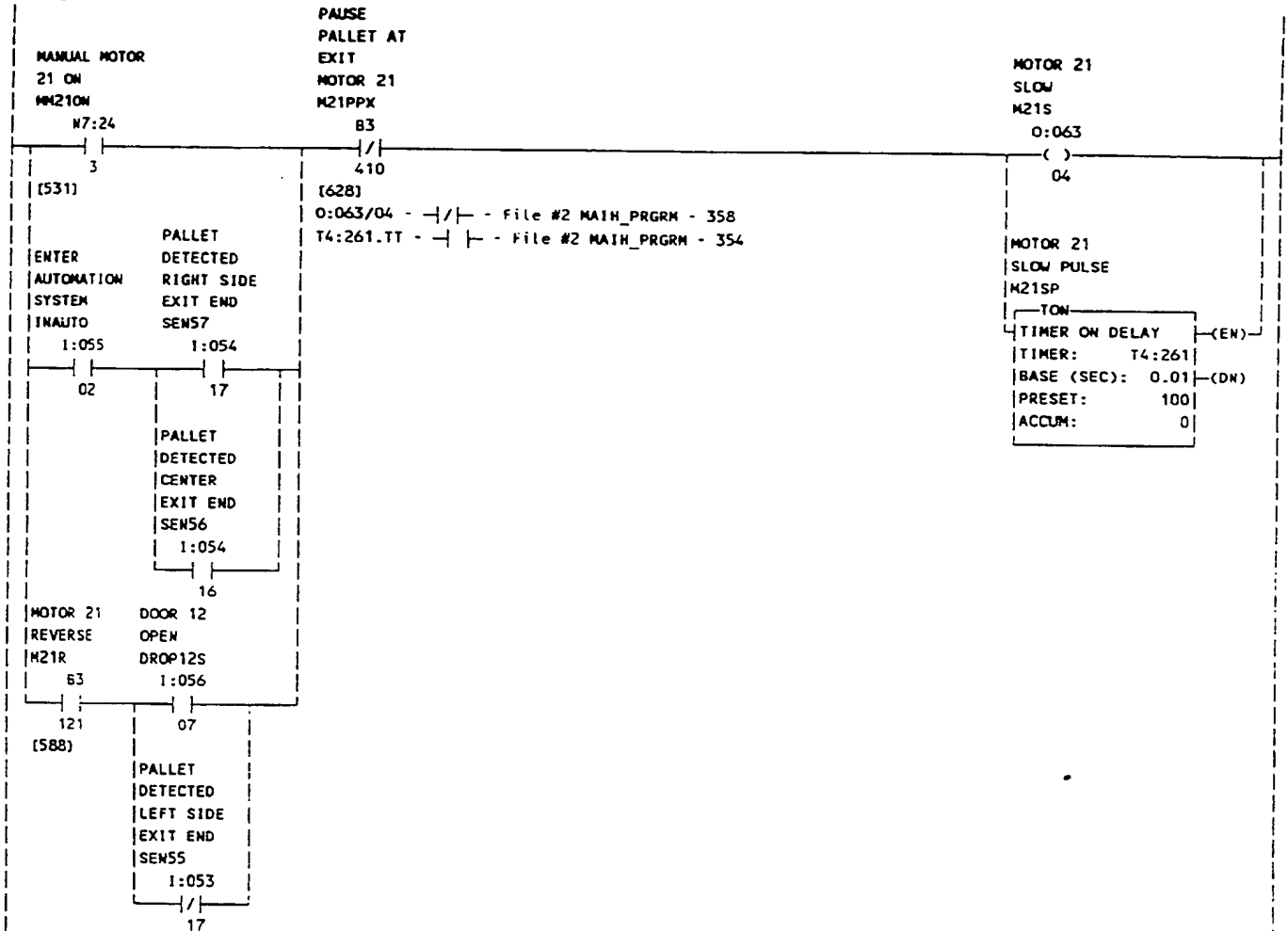
O:062/14 - File #5 FAULTS - 14
 - File #2 MATH_PRGRM - 356
 - File #2 MATH_PRGRM - 355
 T4:221.TT - File #2 MATH_PRGRM - 354
 Rung #356



T4:241.TT - File #2 MATH_PRGRM - 354

315

Rung #357



Rung #358



CS:17.DN - | | - File #2 MAIN_PRGRM 364,365

Rung #364

PALLET
COUNTER
LATCH
PALCNT NRSTCNTR_A
B3 CS:17
100 DN
[360] [363]

NON-RESETABLE
PALLET COUNTER
B
NRSTCNTR_B

CTU
COUNT UP (CU)
COUNTER: C5:18
PRESET: 1000 (DN)
ACCUM: 53

Rung #365

NRSTCNTR_A
C5:17
DN
[365]

NON-RESETABLE
PALLET COUNTER
A
NRSTCNTR_A
C5:17
[RES]

C5:17 - CTU - File #2 MAIN_PRGRM - 363

RES - File #2 MAIN_PRGRM - 365

CS:17.DN - | | - File #2 MAIN_PRGRM - 364

Rung #366

EXLOCK
CHAMBER
PRESSUR AT
ATMOSPHERE
PS6
1:052
0-

CHAMBER VENT 5
CLOSE DELAY
CV5_DLY

TON
TIMER ON DELAY (EN)
TIMER: T4:329
BASE (SEC): 1.0 (DN)
PRESET: 1
ACCUM: 0

T4:329.DN - | | - File #2 MAIN_PRGRM - 367

318

Rung #367

OPEN
EXLOCK
CHAMBER
VENT VALVE
CVS

O:057

(U)

16

CVS_DLY
T4:329

DN

[366]

MANUAL
CONTROL
CHAMBER
VENT VALVE
5 CLOSE
M-CVS-0

N7:4

4

[3]

EXITLOCK
CHAMBER

DOOR 11 GATE VALVE

CLOSED CLOSED

DRCL11S HV12S1

I:056

I:054

/ /

04

/ /

03

BUFFER 4
CHAMBER

DOOR 11 DOOR 10 GATE VALVE

OPEN OPEN CLOSED

DROP11S DROP10S HV11S1

I:056

I:056

I:054

/ /

05

/ /

03

/ /

00

DWELL 6

CHAMBER

GATE VALVE

CLOSED

HV10S1

I:052

/ /

06

DWELL 5

CHAMBER

GATE VALVE

CLOSED

HV9S1

I:040

/ /

03

EXLOCK

CHAMBER

PUMPDOWN DOOR 11 PRESSUR AT

EXIT LOCK CLEAN CYCLE CLOSED ATMOSPHERE

PD-EX-CC DRCL11S PS6

B3

I:056

I:052

/ /

497

/ /

04

/ /

04

[692]

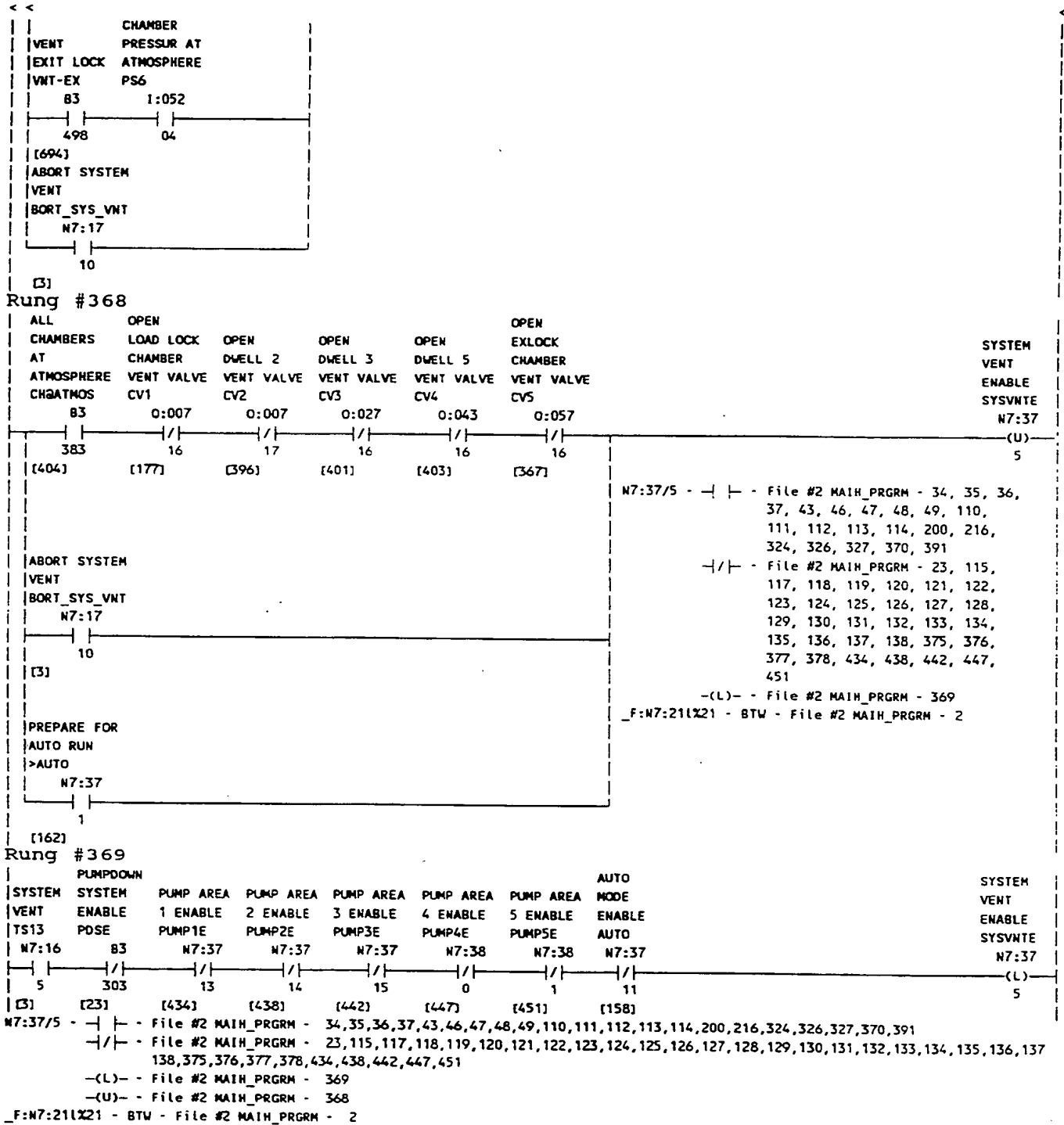
EXLOCK

O:057/16 - / / - File #2 MAIN_PRGRM - 347

File #6 TECH_RUNGS - 0

- / / - File #2 MAIN_PRGRM - 67, 327, 340, 368, 453, 689, 695

-(L) - File #2 MAIN_PRGRM - 346



Rung #370

SYSTEM
VENT
ENABLE
SYSVNTPLSE
N7:37

5
[369]

SYSTEM
VENT
ENABLE
PULSE
SYSVNTPLSE

TON
TIMER ON DELAY
TIMER: T4:286
BASE (SEC): 1.0
PRESET: 180
ACCUM: 0

T4:286 - TON - File #2 MAIN_PRGRM - 370
LEQ - File #2 MAIN_PRGRM - 84,91,98
T4:286.DM - | | - File #2 MAIN_PRGRM - 608

Rung #371

MANUAL HEATER 1
CONTROL CHAMBER
RGA VALVE =<250
1 OPEN MICRONS
M-RGAV1-1 PIR2
N7:7 1:004

5 10

[3]

O:010/13 - | | - File #6 TECH_RUNGS - 7
-(U)- - File #2 MAIN_PRGRM - 34
N7:28/5 - -(U)- - File #2 MAIN_PRGRM - 34
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/1 - -(L)- - File #2 MAIN_PRGRM - 34
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

OPEN RGA
ISOLATION
VALVE 1
RGAV1
O:010

(L)
13

MANUAL RGA
VALVE 1
OPEN
MRGAV1OP
N7:28

(L)
5

MANUAL RGA
VALVE 1
CLOSE
MRGAV1CL
N7:30

(U)
1

Rung #372

MANUAL CHROME
CONTROL CHAMBER
RGA VALVE =<250
2 OPEN MICRONS
M-RGAV2-1 PIR6
N7:7 1:024

6 07

[3]

O:030/13 - | | - File #6 TECH_RUNGS - 7
-(U)- - File #2 MAIN_PRGRM - 35
N7:28/6 - -(U)- - File #2 MAIN_PRGRM - 35
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/2 - -(L)- - File #2 MAIN_PRGRM - 35
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

OPEN RGA
ISOLATION
VALVE 2
RGAV2
O:030

(L)
13

MANUAL RGA
VALVE 2
OPEN
MRGAV2OP
N7:28

(L)
6

MANUAL RGA
VALVE 2 CLOSE
MRGAV2CL
N7:30

(U)
2

Rung #373

MANUAL MAGNETIC
CONTROL CHAMBER
RGA VALVE =<250
3 OPEN MICRONS
M-RGAV3-1 PIR11
N7:7 I:040

7 07

[3]

0:044/13 - | | - File #6 TECH_RUNGS - 7
-(U)- - File #2 MAIN_PRGRM - 36
N7:28/7 - -(U)- - File #2 MAIN_PRGRM - 36
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/3 - -(L)- - File #2 MAIN_PRGRM - 36
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2

OPEN RGA
ISOLATION
VALVE 3
RGAV3
0:044

(L)
13

MANUAL RGA
VALVE 3
OPEN
MRGAV3OP
N7:28

(L)
7
MANUAL RGA
VALVE 3 CLOSE
MRGAV3CL
N7:30
(U)
3

Rung #374

MANUAL EXIT BUFFER
CONTROL CHAMBER
RGA VALVE =<250
4 OPEN MICRONS
M-RGAV4-1 PIR15
N7:7 I:040

8 13

[3]

0:060/13 - | | - File #6 TECH_RUNGS - 7
-(U)- - File #2 MAIN_PRGRM - 37
N7:28/8 - -(U)- - File #2 MAIN_PRGRM - 37
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/4 - -(L)- - File #2 MAIN_PRGRM - 37
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2

OPEN RGA
ISOLATION
VALVE 4
RGAV4
0:060

(L)
13

MANUAL RGA
VALVE 4
OPEN
MRGAV4OP
N7:28

(L)
8
MANUAL RGA
VALVE 4 CLOSE
MRGAV4CL
N7:30
(U)
4

Rung #375

HEATER 1
CHAMBER SYSTEM
=<250 VENT AREA VENT
MICRONS 1 ENABLE ENABLE
PIR2 VENT1E SYSVNT
I:004 N7:37 N7:37

10 6 5

[405] [369]

0:010/06 - | | - File #6 TECH_RUNGS - 7
-|/| - File #2 MAIN_PRGRM - 389,409
-() - File #2 MAIN_PRGRM - 375

OPEN
CAPACITANC
MANOMETER
ISOLATION
VALVE 1
CHV1

0:010

()
06

Rung #376

CHROME
CHAMBER
=<250 VENT AREA VENT
MICRONS 2 ENABLE ENABLE
PIR6 VENT2E SYSVNTE
1:024 N7:37 N7:37
07 7 5

OPEN
CAPACITANC
MANOMETER
ISOLATION
VALVE 2
CMV2

0:030

()
06

0:030/06 - [411] [369]
- | | - File #6 TECH_RUNGS - 7
- | | - File #2 MAIH_PRGRM - 389,416
- () - File #2 MAIH_PRGRM - 376

Rung #377

MAGNETIC
CHAMBER
=<250 VENT AREA VENT
MICRONS 3 ENABLE ENABLE
PIR11 VENT3E SYSVNTE
1:040 N7:37 N7:37
07 8 5

OPEN
CAPACITANC
MANOMETER
ISOLATION
VALVE 3
CMV3

0:044

()
06

0:044/06 - [418] [369]
- | | - File #6 TECH_RUNGS - 7
- | | - File #2 MAIH_PRGRM - 389,423
- () - File #2 MAIH_PRGRM - 377

Rung #378

CARBON
CHAMBER
=<250 VENT AREA VENT
MICRONS 4 ENABLE ENABLE
PIR16 VENT4E SYSVNTE
1:054 N7:37 N7:37
07 9 5

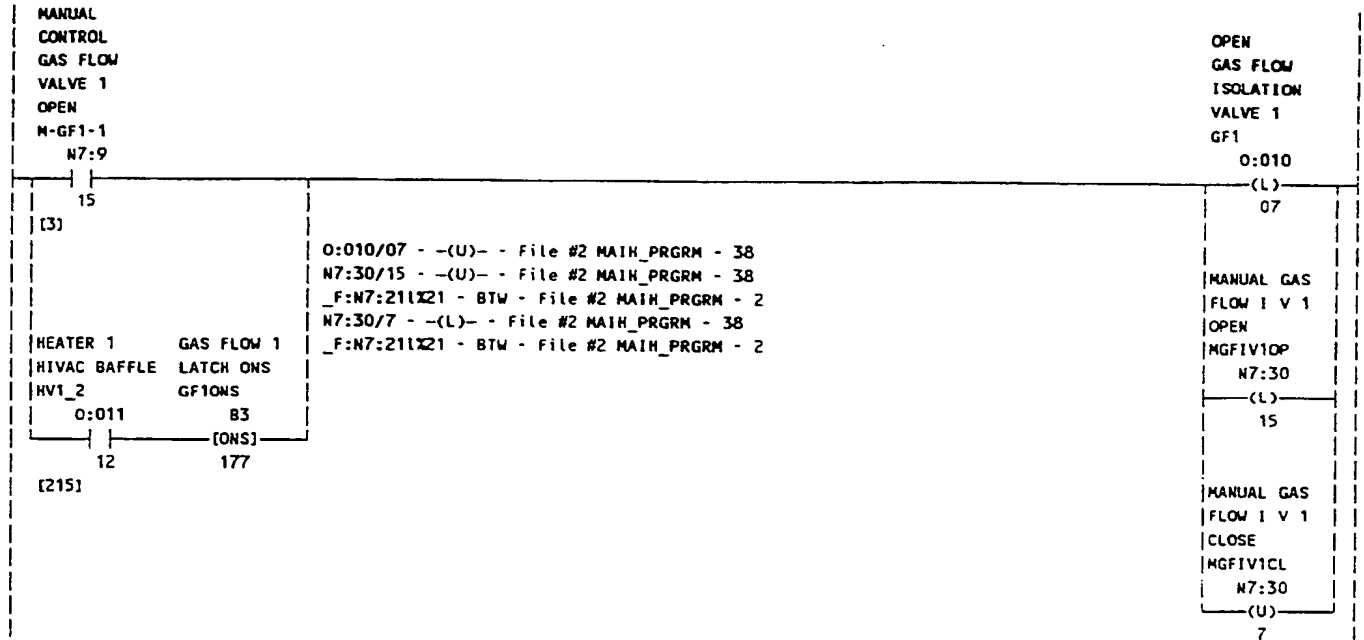
OPEN
CAPACITANC
MANOMETER
ISOLATION
VALVE 4
CMV4

0:060

()
06

0:060/06 - [425] [369]
- | | - File #6 TECH_RUNGS - 7
- | | - File #2 MAIH_PRGRM - 389,428
- () - File #2 MAIH_PRGRM - 378

BASE : Rung #379



324

12

Rung #380

MANUAL CONTROL
GAS FLOW VALVE
2 OPEN
G-GF2-1

N7:10

0

[3]

O:010/10 - -(U)- - File #2 MAIN_PRGRM - 39
N7:31/0 - -(U)- - File #2 MAIN_PRGRM - 39
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/8 - -(L)- - File #2 MAIN_PRGRM - 39
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

OPEN
GAS FLOW
ISOLATION
VALVE 2
GF2

O:010

(L)

10

MANUAL GAS
FLOW I V 2

OPEN

HGFIV2OP

N7:31

(L)

0

MANUAL GAS
FLOW I V 2

CLOSE

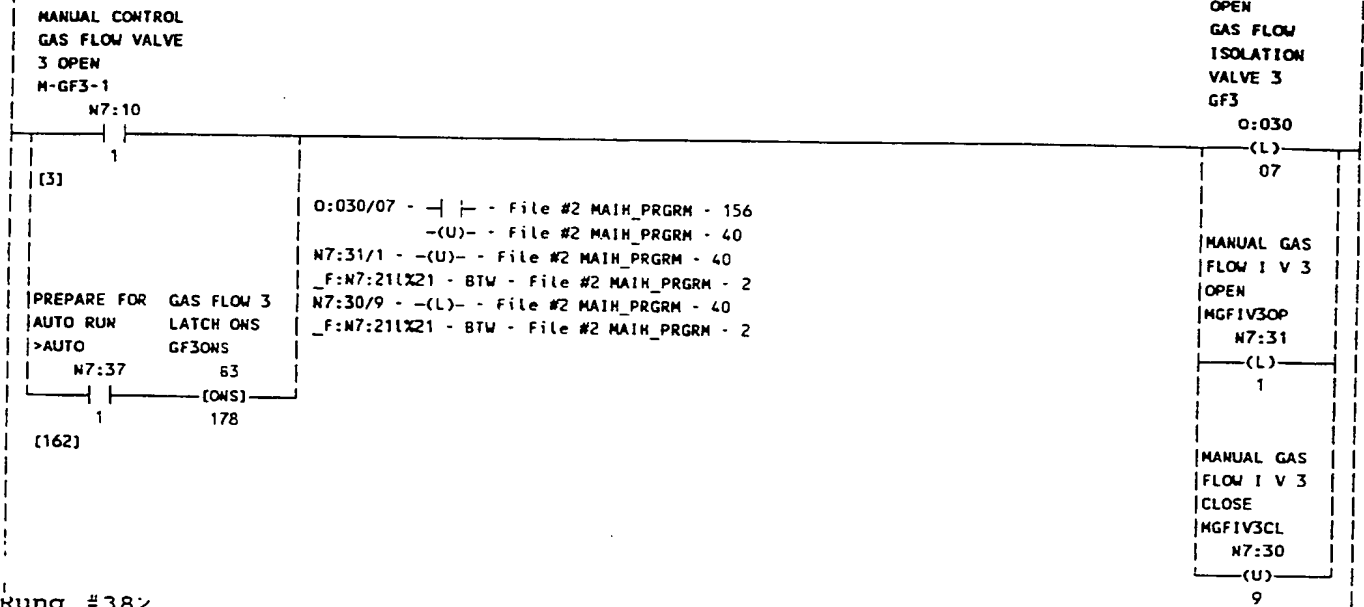
HGFIVZCL

N7:30

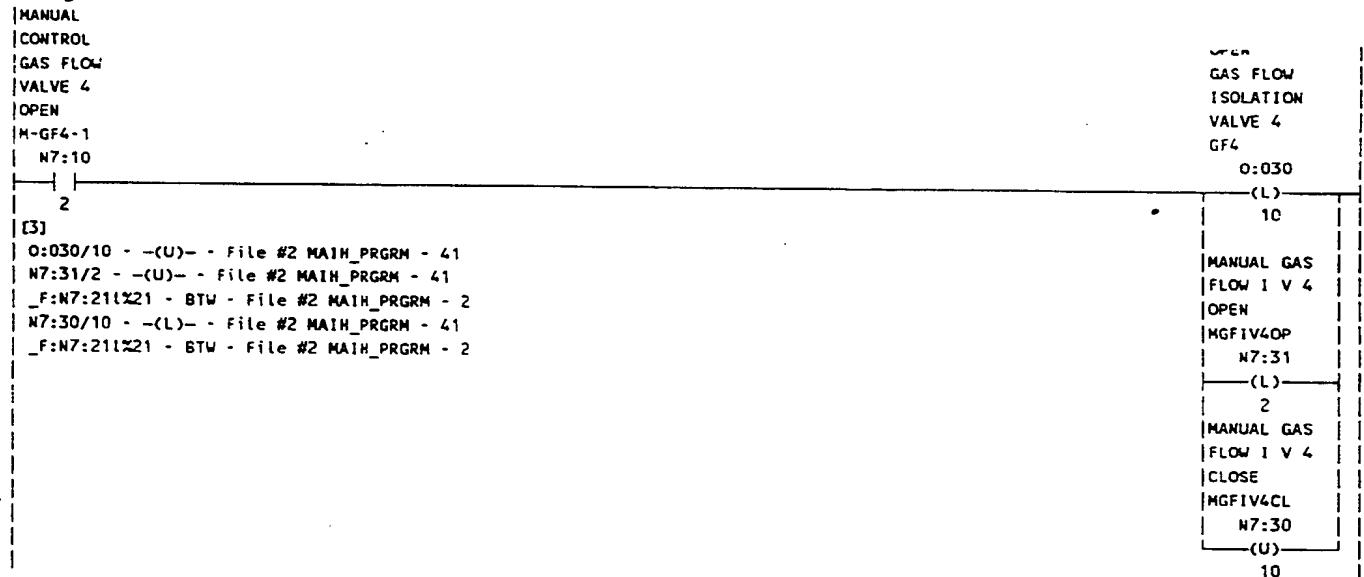
(U)

8

BASE : Rung #381



Rung #382



326

BASE : Rung #383

MANUAL
CONTROL
GAS FLOW
VALVE 5
OPEN
M-GF5-1
N7:10

GAS FLOW
ISOLATION
VALVE 5
GF5

0:044

(L)

07

(3)

0:044/07 - - - File #2 MAIN_PRGRM - 156
-(U)- - File #2 MAIN_PRGRM - 42
N7:31/3 - -(U)- - File #2 MAIN_PRGRM - 42
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/11 - -(L)- - File #2 MAIN_PRGRM - 42
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR GAS FLOW 5
AUTO RUN LATCH ONS
>AUTO GF5ONS

N7:37

83

[ONS]

1

179

[162]

MANUAL GAS
FLOW I V 5
OPEN
MGFIV5OP
N7:31

(L)

3

MANUAL GAS
FLOW I V 5
CLOSE
MGFIV5CL
N7:30

(U)

11

#384

MANUAL
CONTROL
GAS FLOW
VALVE 6
OPEN
M-GF6-1
N7:10

GAS FLOW
ISOLATION
VALVE 6
GF6

0:044

(L)

10

(3)

0:044/10 - -(U)- - File #2 MAIN_PRGRM - 43
N7:31/4 - -(U)- - File #2 MAIN_PRGRM - 43
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/12 - -(L)- - File #2 MAIN_PRGRM - 43
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL GAS
FLOW I V 6
OPEN
MGFIV6OP
N7:31

(L)

4

MANUAL GAS
FLOW I V 6
CLOSE
MGFIV6CL
N7:30

(U)

12

327

BASE : Rung #385

MANUAL
CONTROL
GAS FLOW
VALVE 7
OPEN
M-GF7-1
N7:10

GAS FLOW
ISOLATION
VALVE 7
GF7
O:060

5
[3]

(L)
07

O:060/07 - | | - File #2 MAIN_PRGRM - 156
-(U)- - File #2 MAIN_PRGRM - 44
N7:31/5 - -(U)- - File #2 MAIN_PRGRM - 44
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2
N7:30/13 - -(L)- - File #2 MAIN_PRGRM - 44
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR GAS FLOW 7
AUTO RUN LATCH QNS
>AUTO GF7ONS

MANUAL GAS
FLOW I V 7
OPEN
MGF1V7OP
N7:31

N7:37 B3
1 (ONS) 180

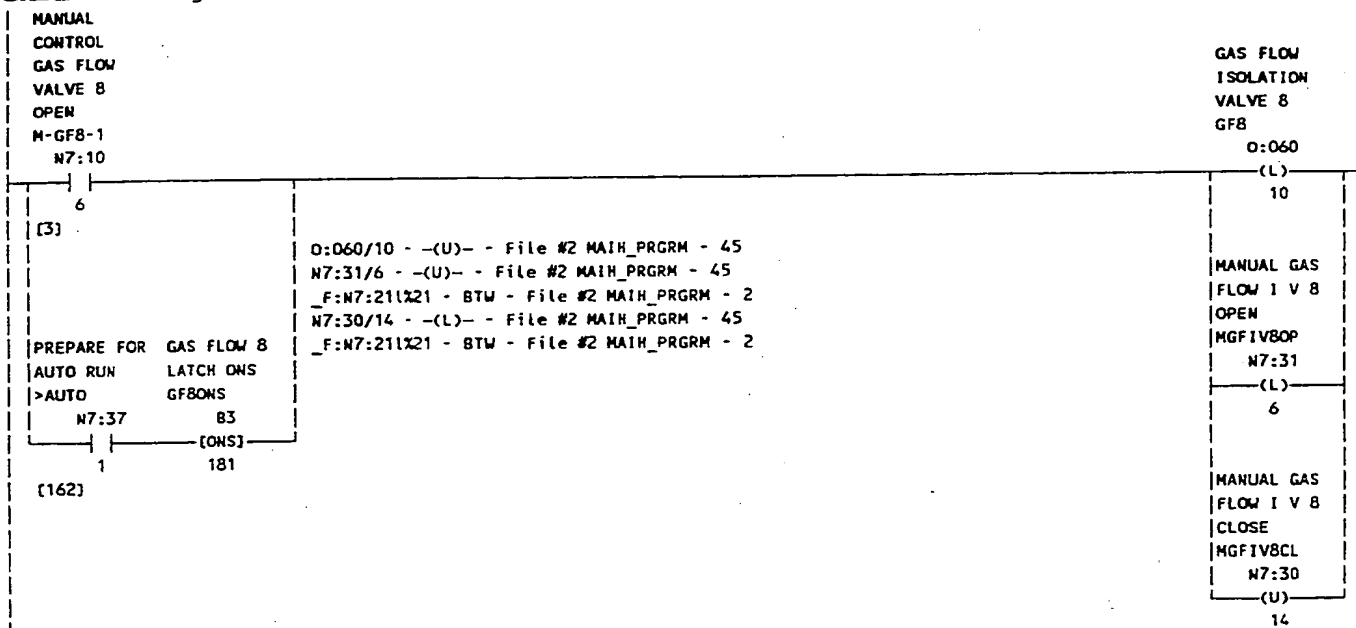
(L)
5

[162]

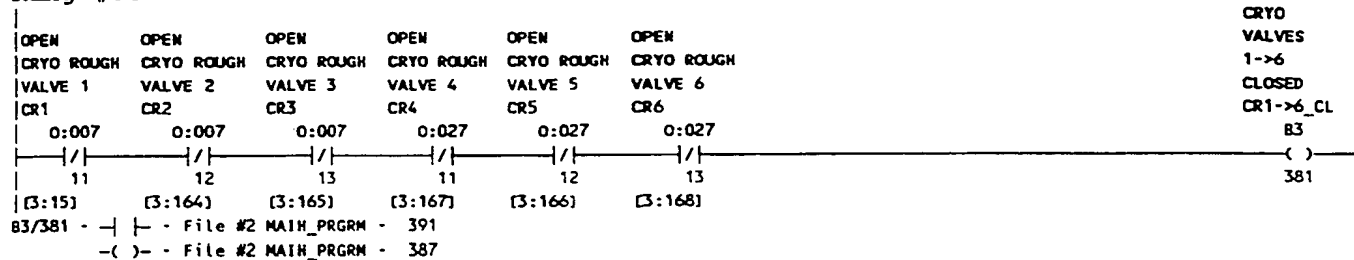
MANUAL GAS
FLOW I V 7
CLOSE
MGF1V7CL
N7:30
(U)
13

328

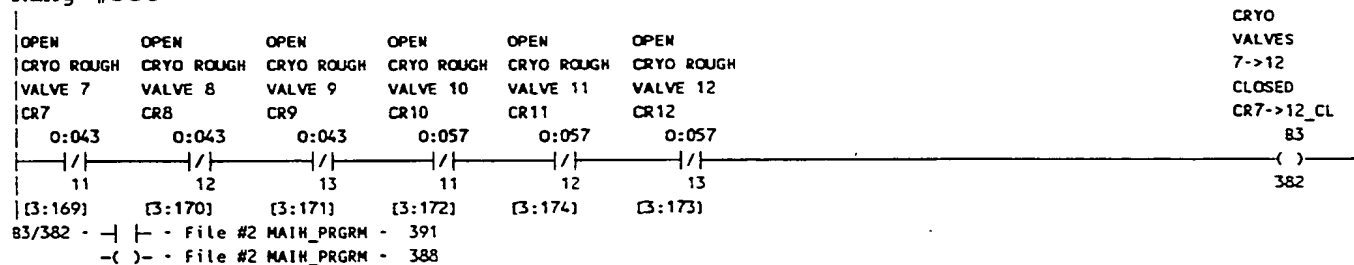
BASE : Rung #386



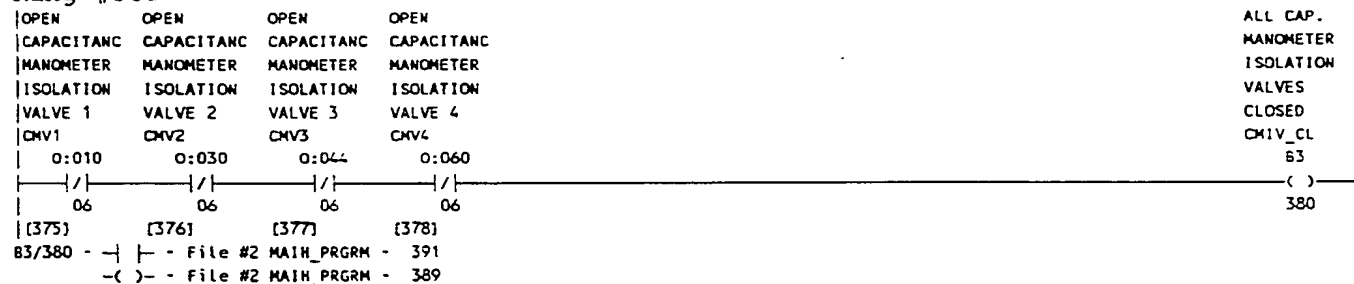
Rung #387



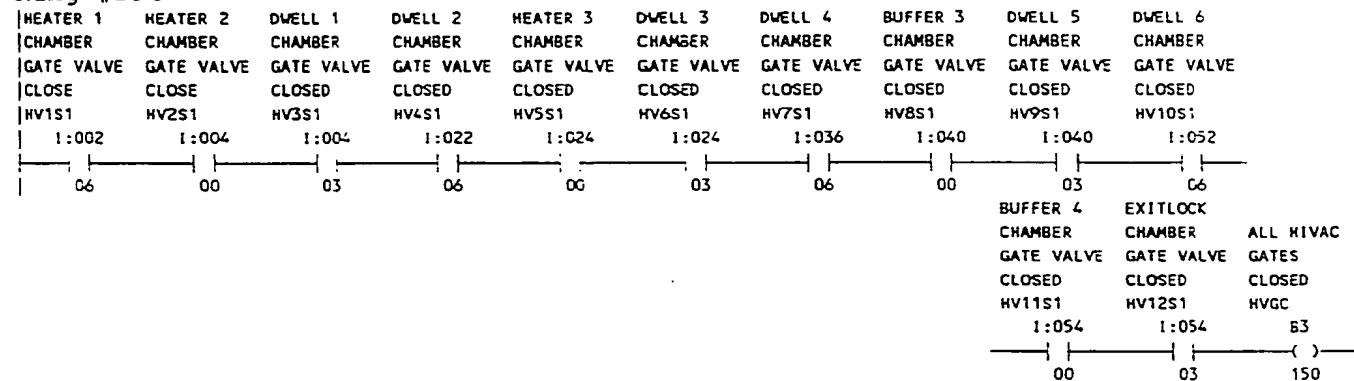
Rung #388



Rung #389

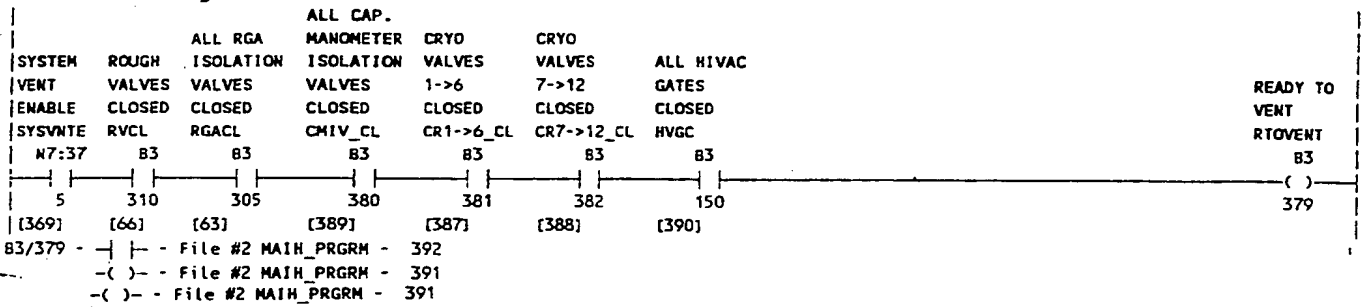


Rung #390

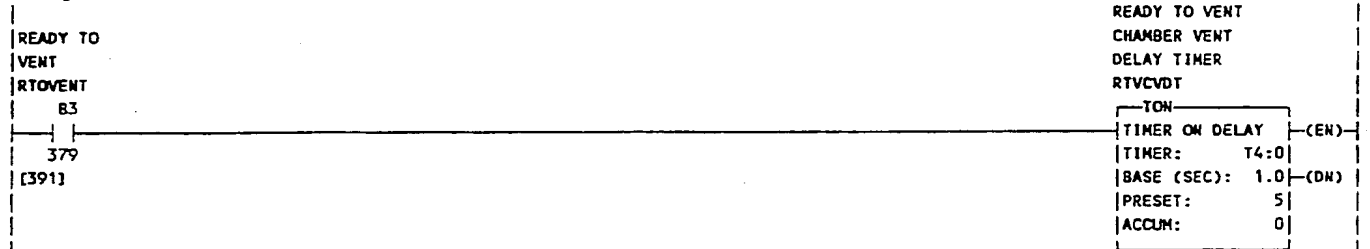


330

BASE : Rung #391

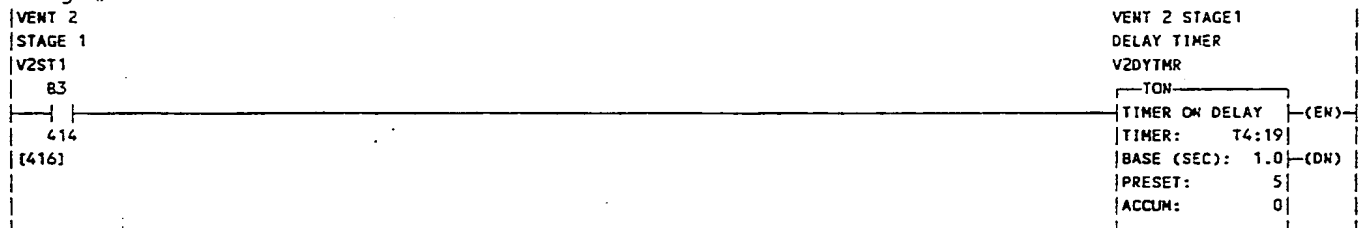


Rung #392



T4:0.DN - | | - File #2 MAIN_PRGRM - 173,346,394,401,403

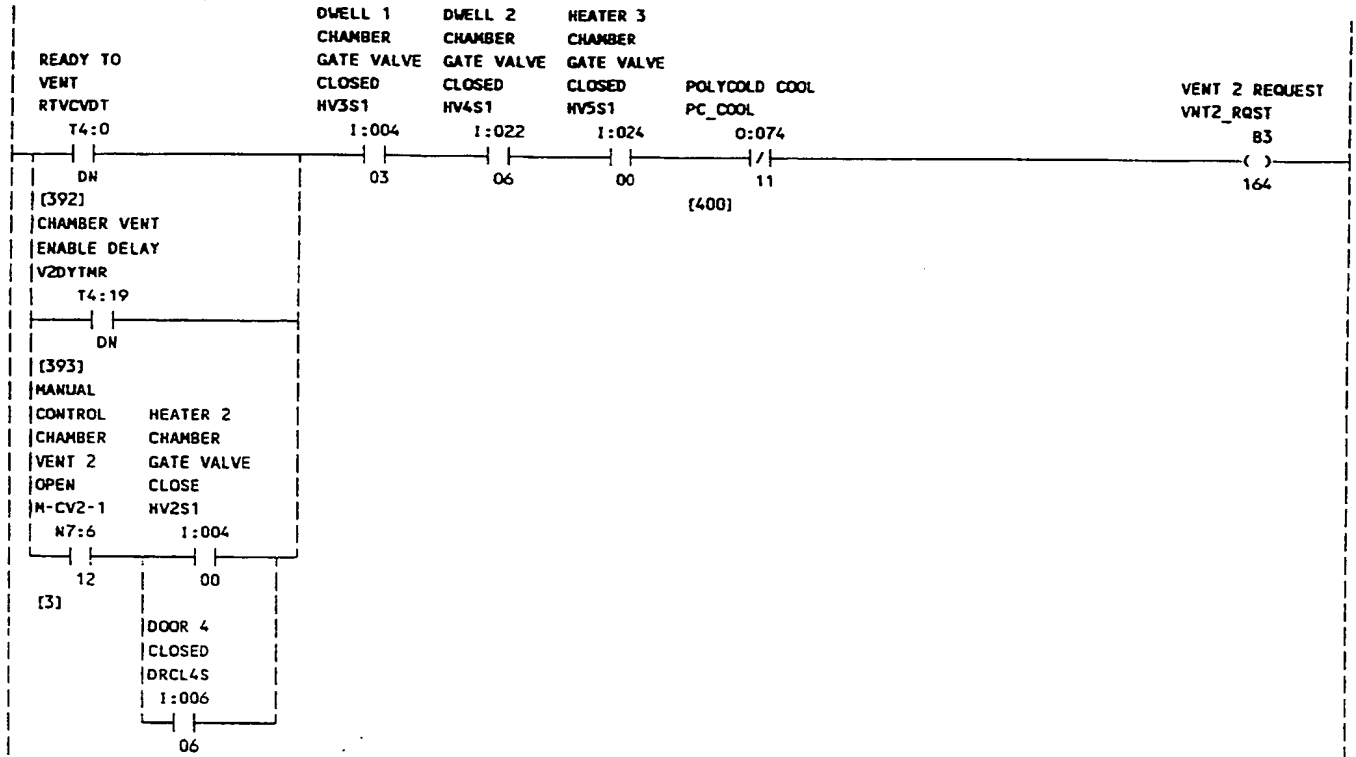
Rung #393



T4:19.DN - | | - File #2 MAIN_PRGRM - 394

331

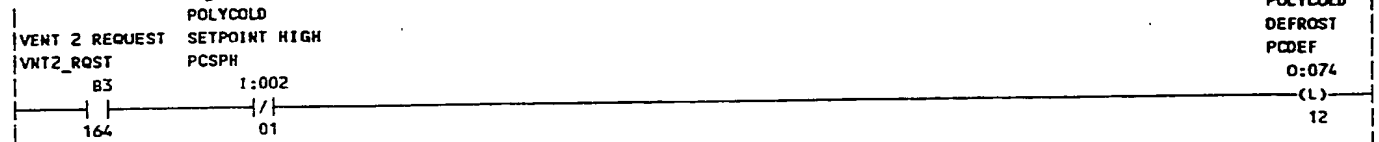
BASE : Rung #394



63/164 - | - File #2 MAIN_PRGRM - 395,396
 -() - File #2 MAIN_PRGRM - 394

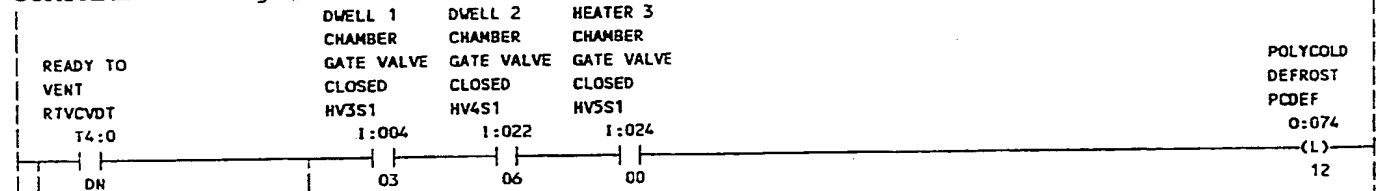
332

BASE : Rung #395



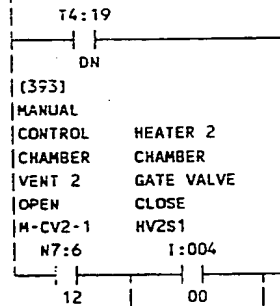
[394]
 O:074/12 - | | - File #2 MAIN_PRGRM - 399
 -|/| - File #2 MAIN_PRGRM - 400
 -(L)- - File #2 MAIN_PRGRM - 395
 -(U)- - File #2 MAIN_PRGRM - 398

COMPARE : Rung #394



O:074/12 - | | - File #2 MAIN_PRGRM - 399
 -|/| - File #2 MAIN_PRGRM - 400
 -(L)- - File #2 MAIN_PRGRM - 395
 -(U)- - File #2 MAIN_PRGRM - 398

CHAMBER VENT
 ENABLE DELAY
 V2DYTMR



[3]

DOOR 4
 CLOSED
 DRCL4S
 1:006
 06

333

BASE : Rung #396

POLYCOLD
VENT 2 REQUEST SETPOINT HIGH
VNT2_RQST PCSPH

83 1:002
164 01

[394]

VENT DELAY
TIMER
VNTDLYTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:80
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 0

T4:80.DN - | - File #2 MAIN_PRGRM - 397

COMPARE : Rung #395

POLYCOLD
DEFROST
PCDEF
0:074

12

[395]

VENT DELAY
TIMER
VNTDLYTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:80
BASE (SEC): 1.0 (DN)
PRESET: 180
ACCUM: 0

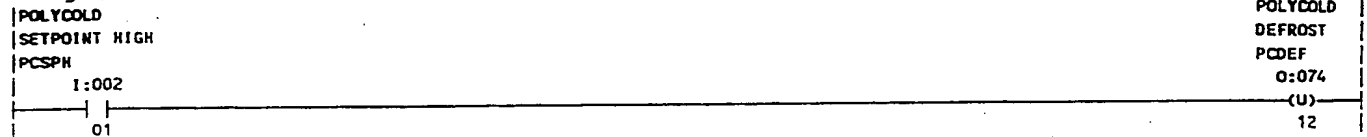
T4:80 - TON - File #2 MAIN_PRGRM - 396

T4:80.DN - | - File #2 MAIN_PRGRM - 397

334

-(U)- - File #2 MAIN_PRGRM - 31

Rung #397



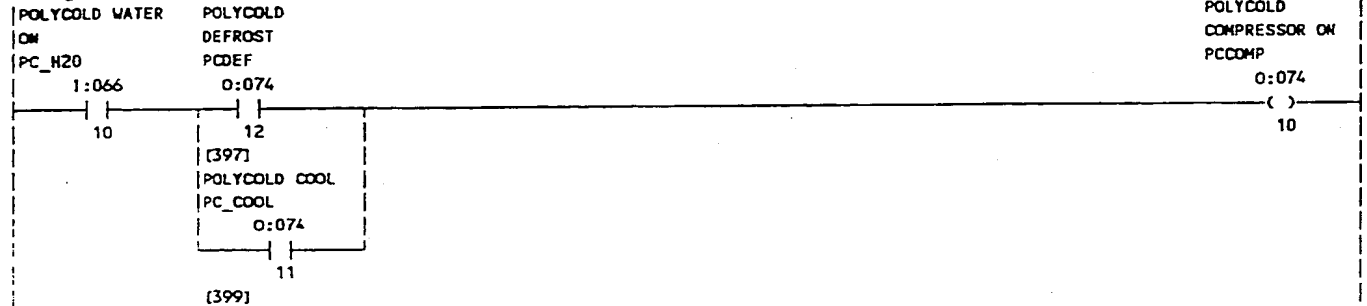
O:074/12 - | | - File #2 MAIN_PRGRM - 395,398

-|/ - File #2 MAIN_PRGRM - 399

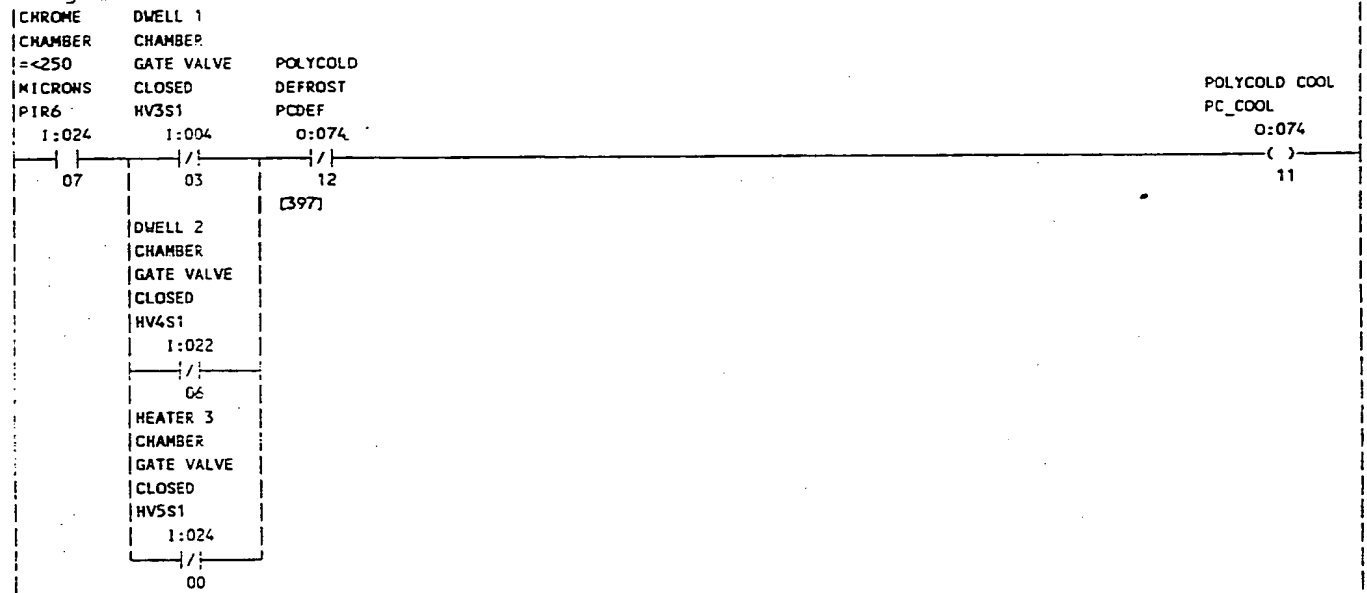
-(L) - File #2 MAIN_PRGRM - 394

-(U) - File #2 MAIN_PRGRM - 397

Rung #398



Rung #399



O:074/11 - | | - File #2 MAIN_PRGRM - 398

-() - File #2 MAIN_PRGRM - 399

Rung #400

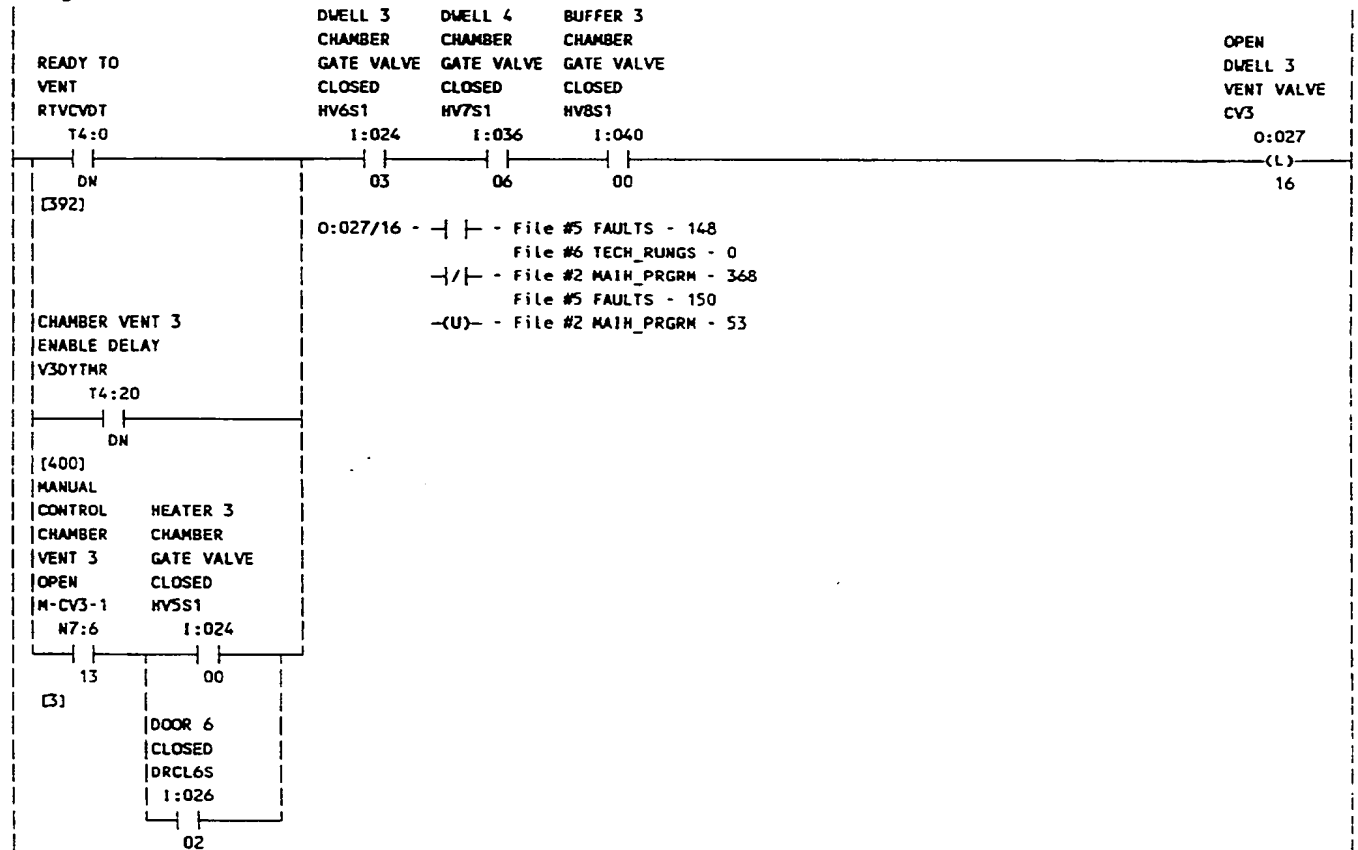
VENT 3
STAGE 1
V3ST1

B3
416
[423]

VENT 3 STAGE1
DELAY TIMER
V3DYTHR

TIMER ON DELAY (EN)
TIMER: T4:20
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 0

T4:20.DN - | | - File #2 MAIN_PRGRM - 401
Rung #401



Rung #402

VENT 4
STAGE 1
V4ST1

B3
418
[428]

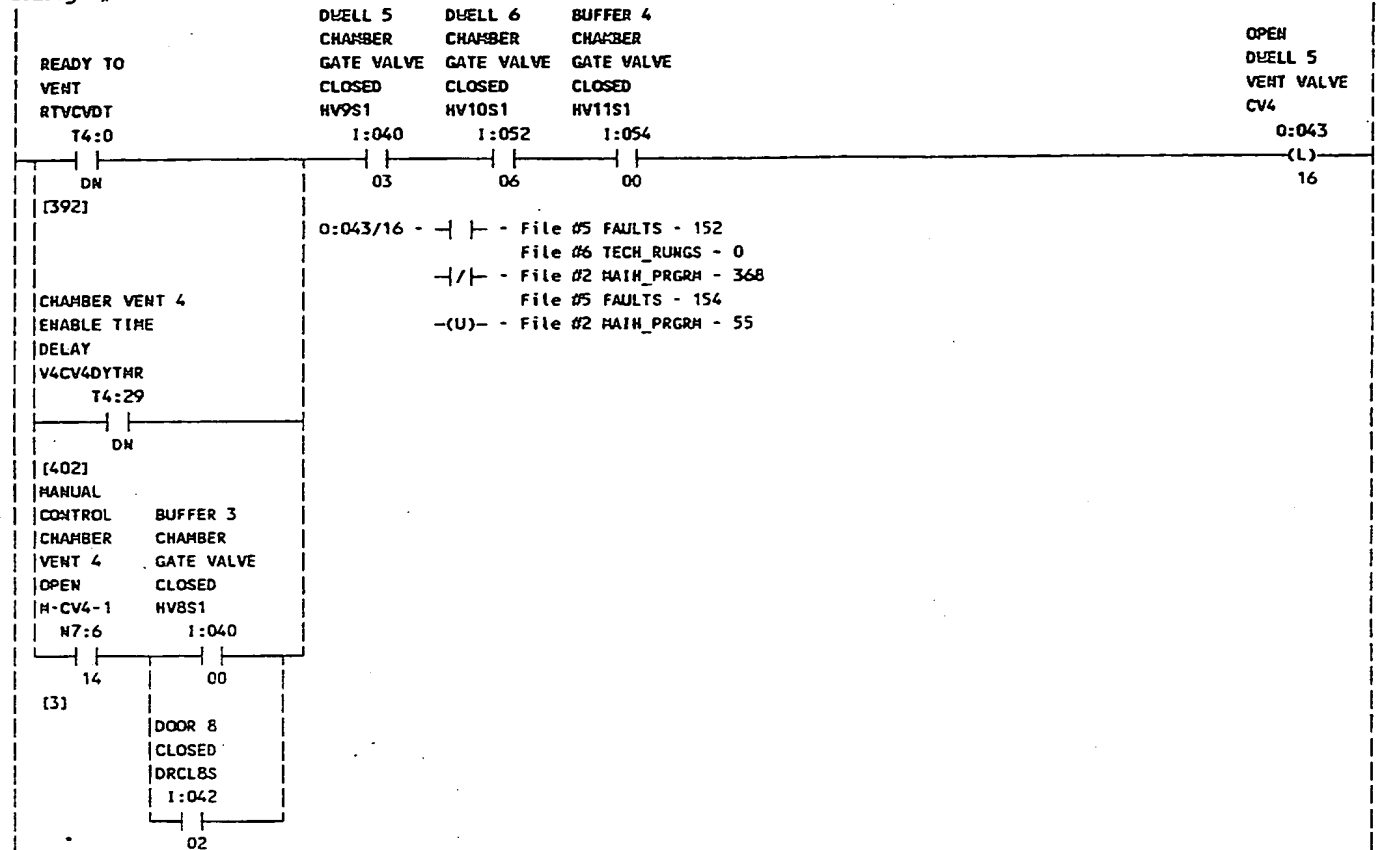
VENT 4 STAGE1
VENT 4 DELAY
TIMER
V4CV4DYTHR

TIMER ON DELAY (EN)
TIMER: T4:29
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 0

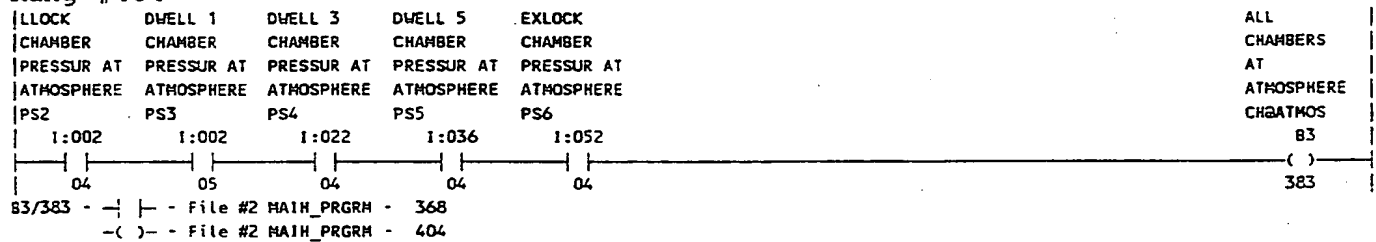
T4:29.DN - | | - File #2 MAIN_PRGRM - 403

336

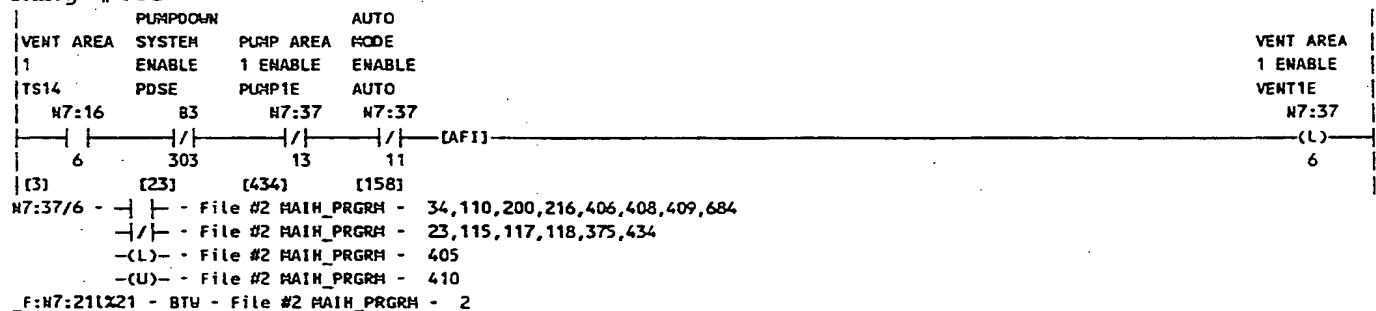
Rung #403



Rung #404



Rung #405



N7:37/13 - | | - File #2 MAIN_PRGRM - 26,27,105,167,183,200,216,408,435,436,455
 -|/| - File #2 MAIN_PRGRM - 369,405
 -(L)- - File #2 MAIN_PRGRM - 434
 -(U)- - File #2 MAIN_PRGRM - 437
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #435

PUMP AREA VENT AREA

1 ENABLE ACTIVE

PUMP1E VNTACT

N7:37 83

| | | |
13 343

[434]

PUMP SECTION 1

TIMER

PMP1TMR

TON

TIMER ON DELAY (EN)

TIMER: T4:256

BASE (SEC): 1.0 (DN)

PRESET: 600

ACCUM: 0

T4:256.DN - | | - File #2 MAIN_PRGRM - 609

Rung #436

	ENABLE CRYO	ENABLE CRYO	OPEN LOAD LOCK					LLOCK CHAMBER ROUGH	
PUMP AREA	COMPRESSOR	COMPRESSOR	CHAMBER	DOOR 1	DOOR 3	DOOR 4	VALVE		
1 ENABLE	1	2	VENT VALVE	CLOSED	OPEN	CLOSED	CLOSED		
PUMP1E	CY1	CY2	CV1	DRCL1S	DROP3S	DRCL4S	RVS1		
N7:37	0:010	0:010	0:007	1:006	1:006	1:006	1:002		

			/						
13	04	05	16	00	05	06	15		

[437] (26) (27) [177]

83/422 - | | - File #2 MAIN_PRGRM - 68,115,117,118,437

-() - File #2 MAIN_PRGRM - 436

PUMP 1

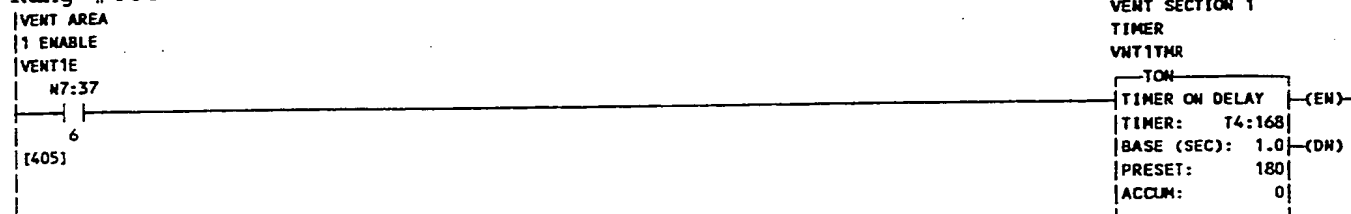
STAGE 1

P1ST1

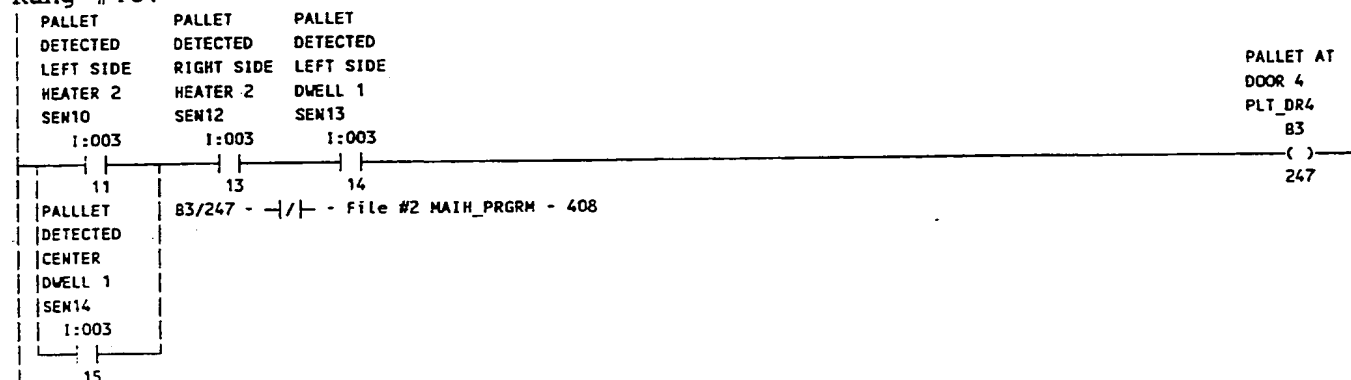
83

422

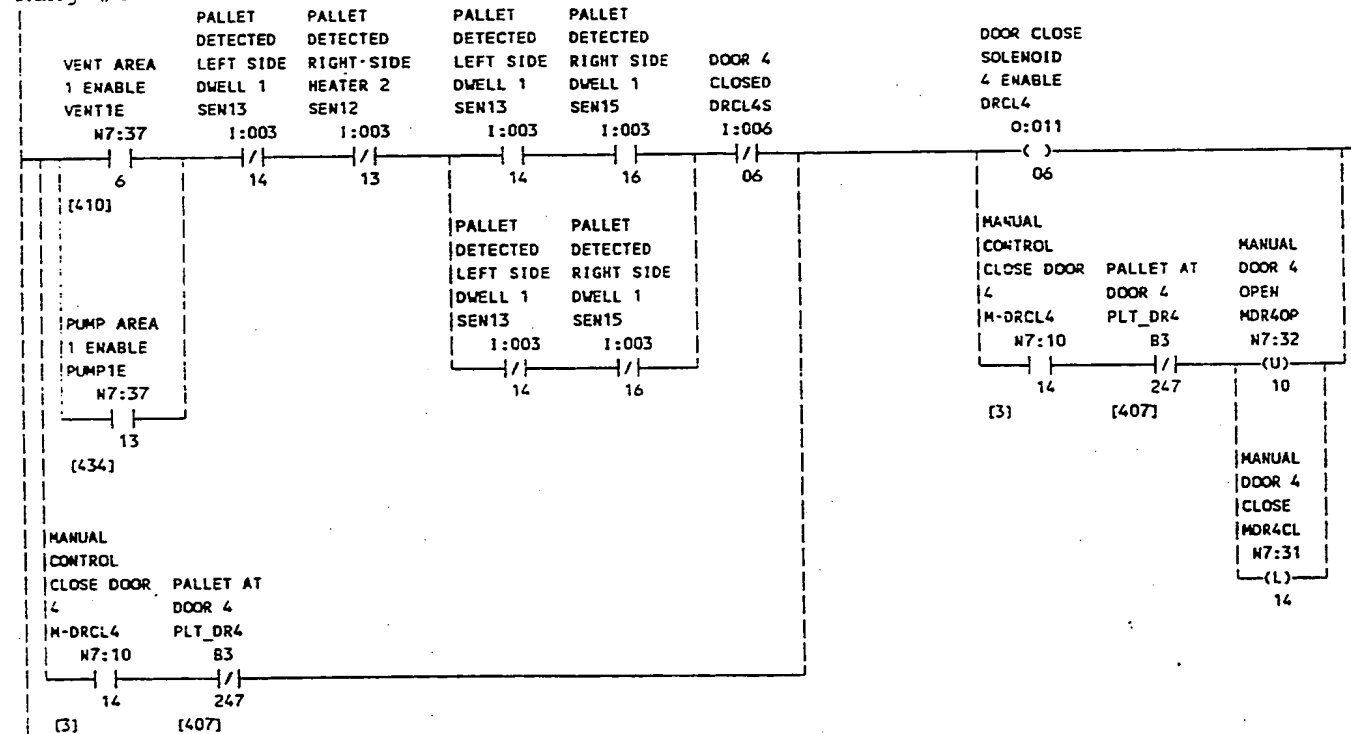
VENT SECTION 1
TIMER
VNT1THR



Rung #407



Rung #408

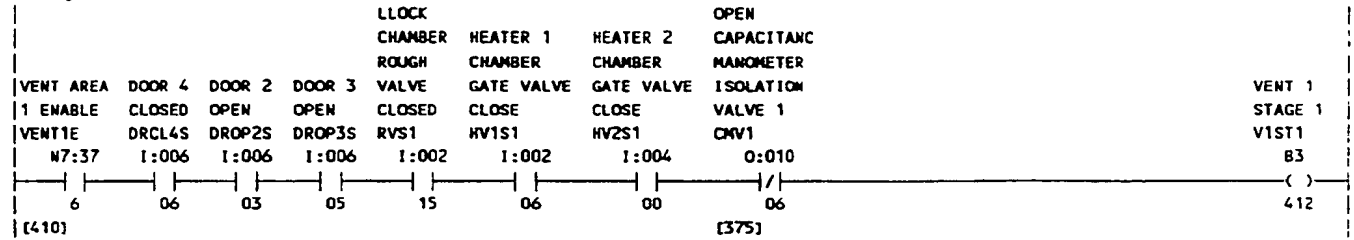


0:011/06 - 1 1 - File #5 FAULTS - 23

339

File #6 TECH_RUNGS -
 -() - File #2 MAIN_PRGRM - 408
 N7:32/10 - (L) - File #2 MAIN_PRGRM - 415
 -(U) - File #2 MAIN_PRGRM - 408
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:31/14 - (L) - File #2 MAIN_PRGRM - 408
 -(U) - File #2 MAIN_PRGRM - 415
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #409



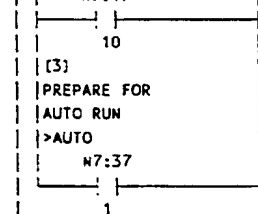
B3/412 - | - File #2 MAIN_PRGRM - 171,410
 -() - File #2 MAIN_PRGRM - 409

Rung #410

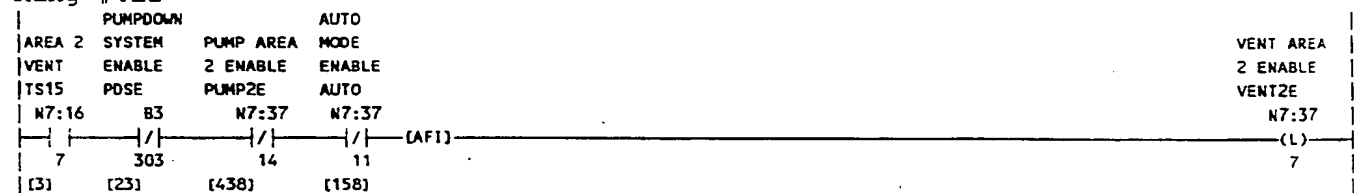


N7:37/6 - | - File #2 MAIN_PRGRM - 34, 110, 200, 216, 406, 408, 409, 684
 -|/ - File #2 MAIN_PRGRM - 23, 115, 117, 118, 375, 434
 -(L) - File #2 MAIN_PRGRM - 405
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

ABORT SYSTEM
 VENT
 BORT_SYS_VNT
 N7:17



Rung #411



N7:37/7 - | - File #2 MAIN_PRGRM - 35,111,229,412,414,415,416
 -|/ - File #2 MAIN_PRGRM - 23,117,118,119,120,121,122,123,124,376,438
 -(L) - File #2 MAIN_PRGRM - 411
 -(U) - File #2 MAIN_PRGRM - 417

340

F:M7:211X21 - 8TW - File #2 MAIN_PRGRA 2

Rung #412

VENT AREA

2 ENABLE

VENT2E

N7:37

7

[411]

VENT SECTION 2

TIMER

VNT2TMR

(ON)	(EN)
TIMER ON DELAY	
TIMER: T4:199	
BASE (SEC): 1.0	(DN)
PRESET: 300	
ACCUM: 0	

T4:199.DN - | | - File #2 MAIN_PRGRM - 608

Rung #413

PALLET CENTER BUFFER 2 SEN23	PALLET DETECTED RIGHT SIDE HEATER 3 SEN24	PALLET DETECTED LEFT SIDE DWELL 3 SEN25
---------------------------------------	---	---

1:023

1:023

1:023

07

10

11

PALLET
DETECTED
CENTER
DWELL 3
SEN26

1:023

12

83/249 - | | - File #2 MAIN_PRGRM - 414, 420

PALLET AT
DOOR 5 AND 6
PLT_DR5,6
83
249

Rung #414

VENT AREA 2 ENABLE VENT2E	PALLET DETECTED LEFT SIDE HEATER 3 SEN22	PALLET DETECTED RIGHT SIDE HEATER 3 SEN24	PALLET DETECTED LEFT SIDE DWELL 3 SEN25	PALLET DETECTED RIGHT SIDE DWELL 3 SEN27	DOOR 5 CLOSED DRCL5S 1:026
---------------------------------	--	---	---	--	-------------------------------------

N7:37

1:023

1:023

1:023

1:023

1:026

7

06

10

11

13

00

[411]

PUMP AREA
2 ENABLE
PUMP2E

N7:37

14

[438]

PALLET DETECTED LEFT SIDE DWELL 3 SEN25	PALLET DETECTED RIGHT SIDE DWELL 3 SEN27
---	--

1:023

1:023

11

13

DOOR CLOSE
SOLENOID
5 ENABLE
DRCL5

0:031

00

MANUAL
CONTROL
CLOSE DOOR
5
M-DRCL5

N7:10

15

[3]

PUMP AREA
5 ENABLE
PUMP5E

N7:38

1

[451]

MANUAL
DOOR 5
OPEN
MORSOP

N7:32

(U)

11

MANUAL
DOOR 5
CLOSE
MORSCL

N7:31

(L)

15

MANUAL
CONTROL
CLOSE DOOR
5
M-DRCL5

N7:10

15

[3]

PALLET AT
DOOR 5 AND 6
PLT_DR5,6

83

249

[413]

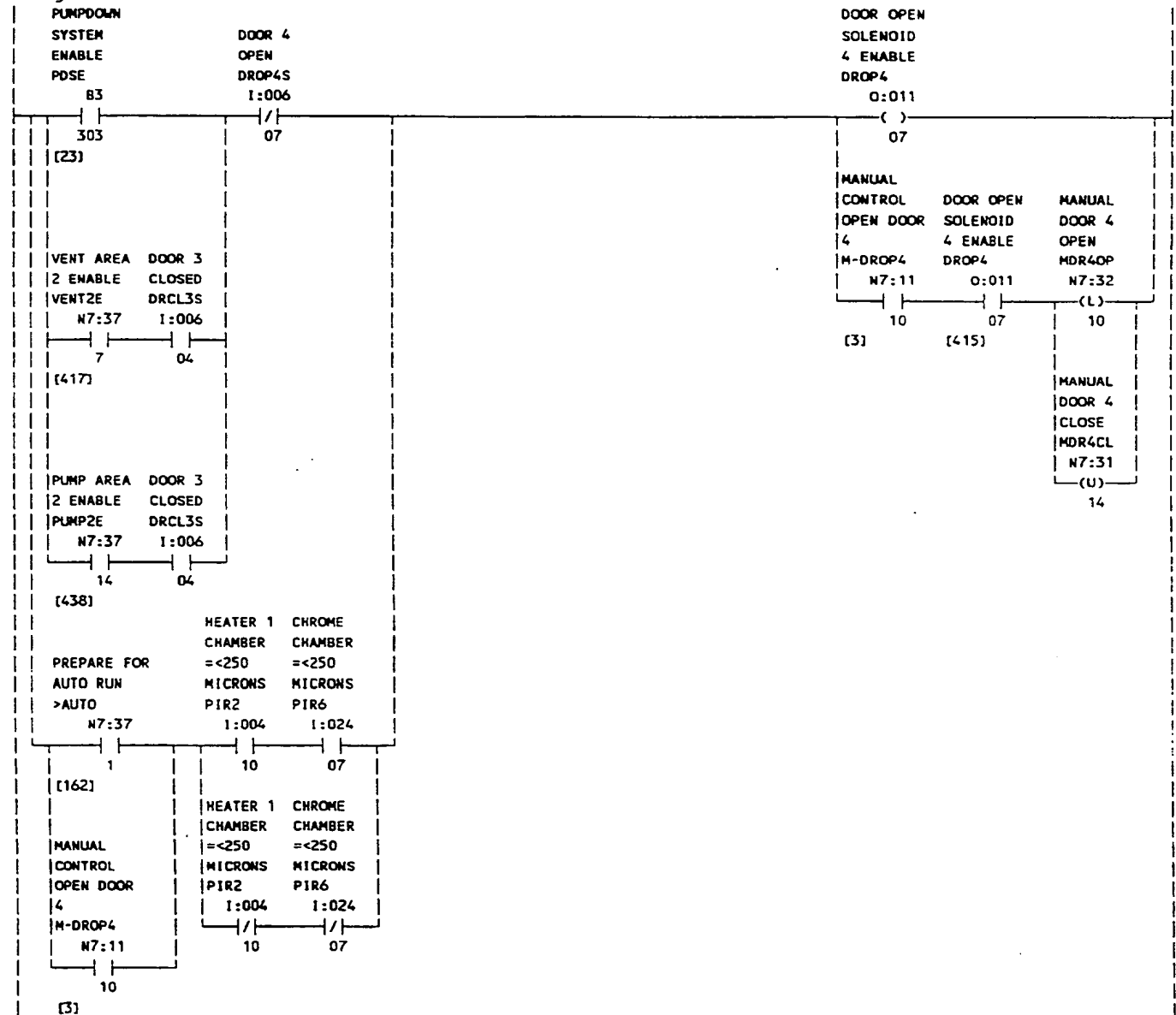
341

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0:031/00 - | | - File #5 FAULTS - 2.
                File #6 TECH_RUNGS - 2
                - ( ) - File #2 MATH_PRGRM - 414
N7:32/11 - (L)- File #2 MATH_PRGRM - 46
                -(U)- File #2 MATH_PRGRM - 414
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2
N7:31/15 - (L)- File #2 MATH_PRGRM - 414
                -(U)- File #2 MATH_PRGRM - 46
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

```

Rung #415

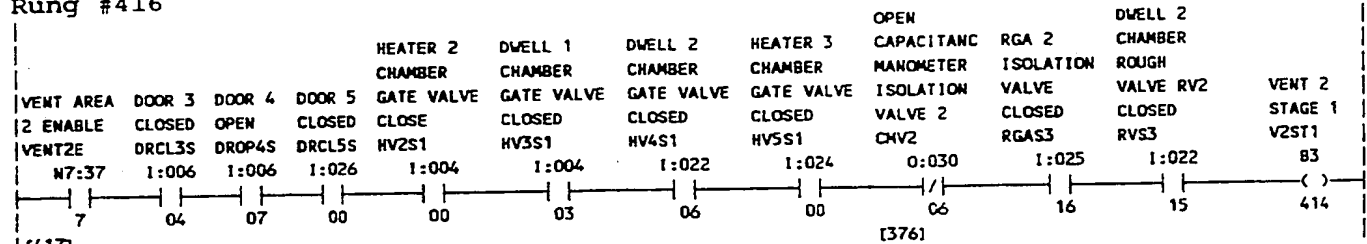


0:011/07 - | | - File #2 MAIN_PRGRM - 415
File #5 FAULTS - 47

342

File #6 TECH_RUNGS 2
 -() - File #2 MAIN_PRGRM - 415
 N7:32/10 - (L) - File #2 MAIN_PRGRM - 415
 -(U) - File #2 MAIN_PRGRM - 408
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:31/14 - (L) - File #2 MAIN_PRGRM - 408
 -(U) - File #2 MAIN_PRGRM - 415
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #416



B3/414 - | | - File #2 MAIN_PRGRM - 393,417
 -() - File #2 MAIN_PRGRM - 416

Rung #417



[416]

N7:37/7 - | | - File #2 MAIN_PRGRM - 35, 111, 229, 412, 414, 415, 416
 -|/| - File #2 MAIN_PRGRM - 23, 117, 118, 119, 120, 121, 122, 123, 124,
 376, 438
 -(L) - File #2 MAIN_PRGRM - 411
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

ABORT SYSTEM

VENT

BORT_SYS_VNT

N7:17

10

[3]

PREPARE FOR

AUTO RUN

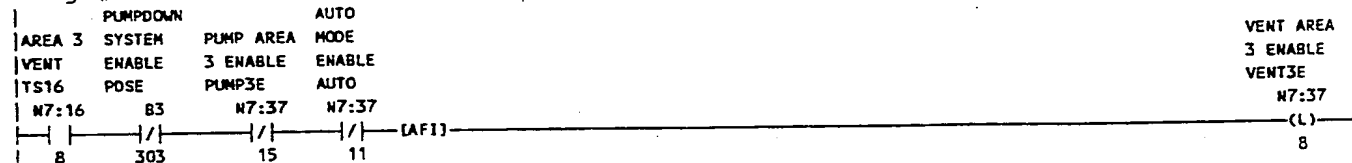
>AUTO

N7:37

1

[162]

Rung #418



[3]

N7:37/8 - | | - File #2 MAIN_PRGRM - 36,43,112,419,420,422,423
 -|/| - File #2 MAIN_PRGRM - 23,125,126,127,128,129,130,377,442
 -(L) - File #2 MAIN_PRGRM - 418
 -(U) - File #2 MAIN_PRGRM - 424

F:N7:211X21 - BTW - File #2 MAIN_PRGM 2

Rung #419

VENT AREA
3 ENABLE
VENT3E

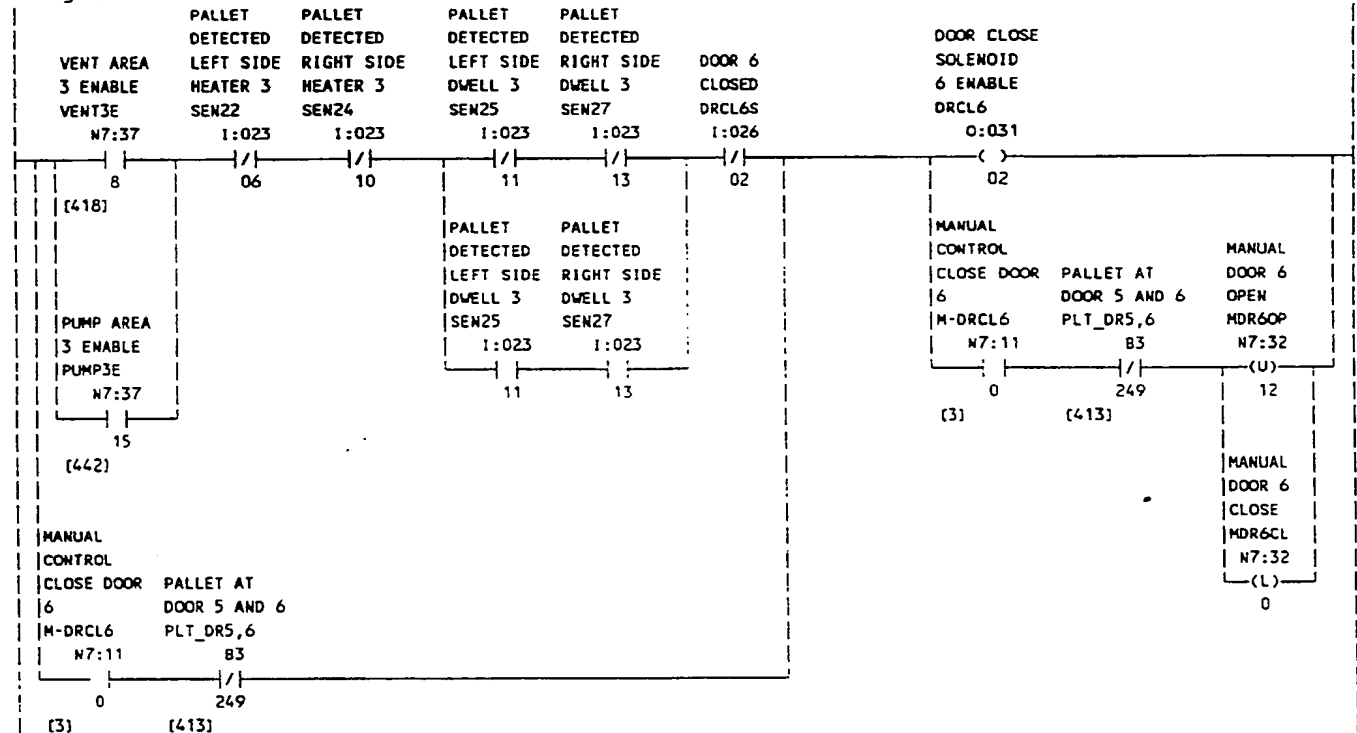
N7:37
8
[418]

VENT SECTION 3
TIMER
VNT3TMR

TOM
TIMER ON DELAY (EN)
TIMER: T4:242
BASE (SEC): 1.0 (DN)
PRESET: 300
ACCU: 0

T4:242.DW - | - File #2 MAIN_PRGM - 608

Rung #420



0:031/02 - | - File #5 FAULTS - 27

File #6 TECH_RUNGS - 2

-() - File #2 MAIN_PRGM - 420

N7:32/12 - -(L) - File #2 MAIN_PRGM - 47

-(U) - File #2 MAIN_PRGM - 420

F:N7:211X21 - BTW - File #2 MAIN_PRGM - 2

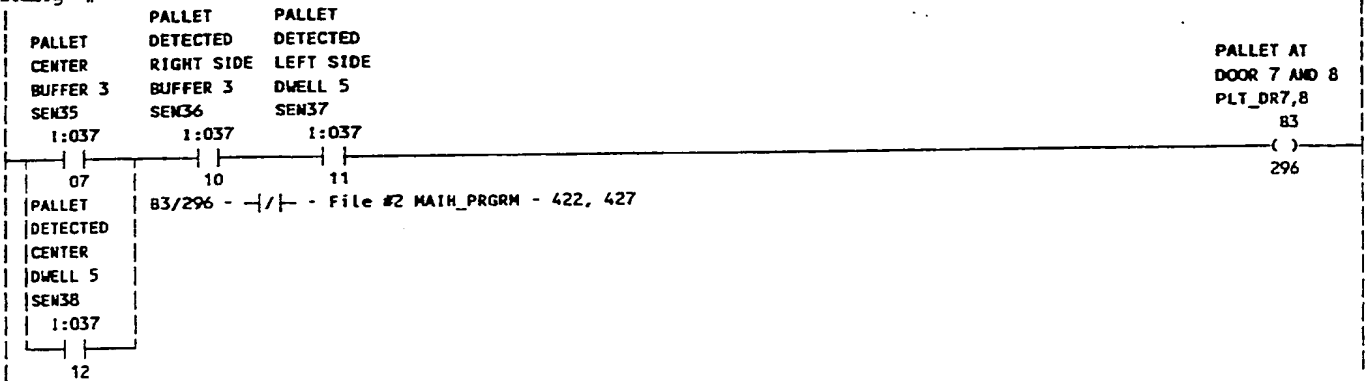
N7:32/0 - -(L) - File #2 MAIN_PRGM - 420

-(U) - File #2 MAIN_PRGM - 47

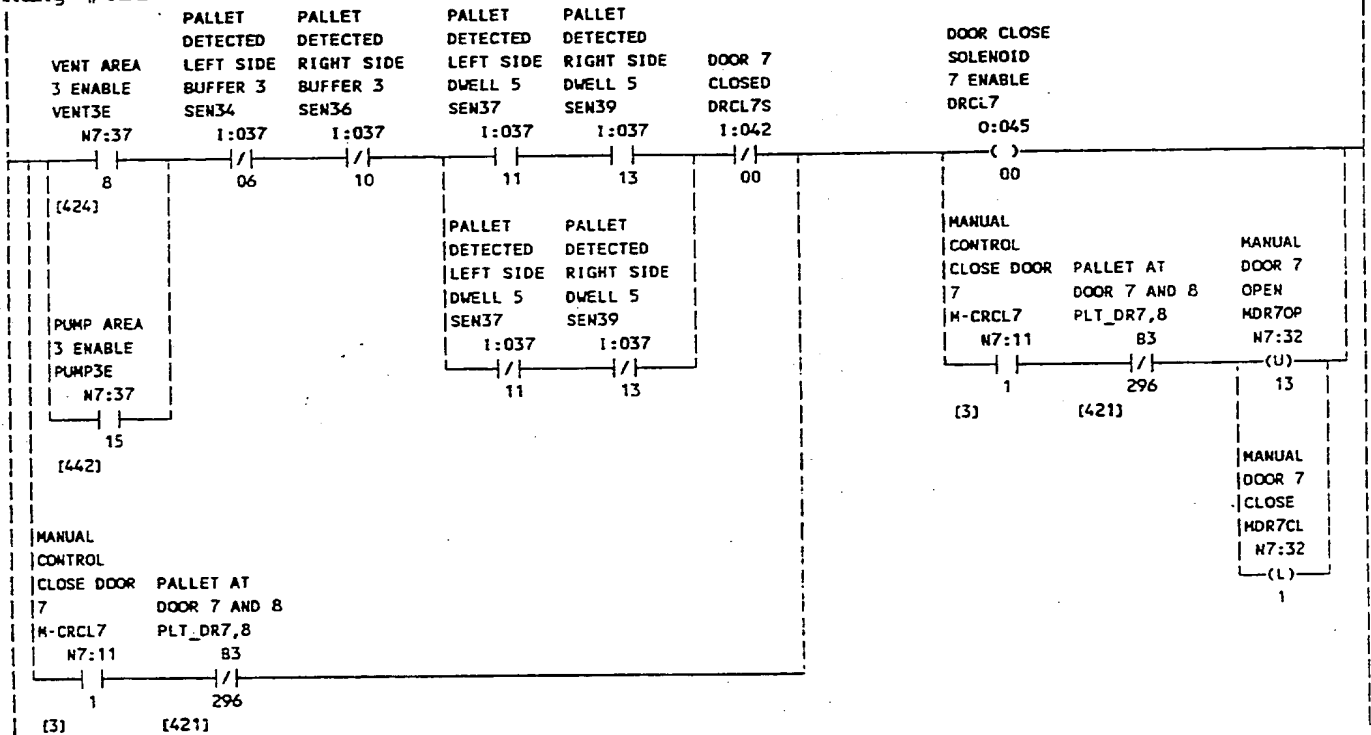
F:N7:211X21 - BTW - File #2 MAIN_PRGM - 2

344

Rung #421

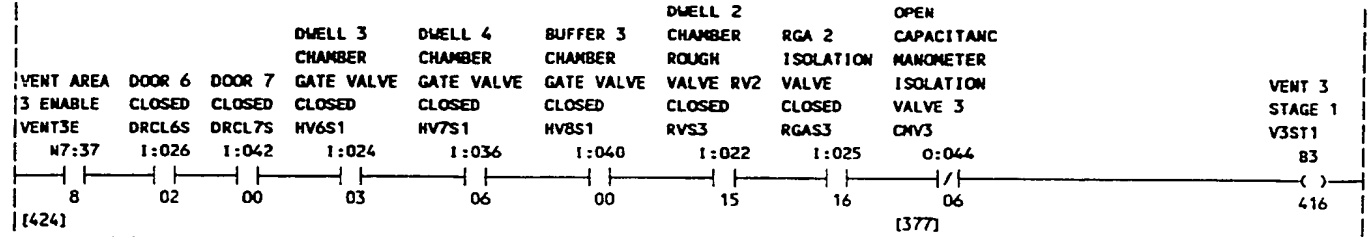


Rung #422



O:045/00 - - - File #5 FAULTS - 29
 File #6 TECH_RUNGS - 3
 - () - File #2 MAIN_PRGRM - 422
 N7:32/13 - - (L) - File #2 MAIN_PRGRM - 48
 - (U) - File #2 MAIN_PRGRM - 422
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:32/1 - - (L) - File #2 MAIN_PRGRM - 422
 - (U) - File #2 MAIN_PRGRM - 48
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #423



B3/416 - | | - File #2 MAIN_PRGRM - 400,424
 -() - File #2 MAIN_PRGRM - 423

Rung #424



[423]

N7:37/8 - | | - File #2 MAIN_PRGRM - 36, 43, 112, 419, 420, 422, 423
 -|/| - File #2 MAIN_PRGRM - 23, 125, 126, 127, 128, 129, 130, 377, 442
 -(L)- File #2 MAIN_PRGRM - 418
 _F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

ABORT SYSTEM

VENT

BORT_SYS_VNT

N7:17

10

[3]

PREPARE FOR

AUTO RUN

->AUTO

N7:37

1

[162]

Rung #425



N7:37/9 - | | - File #2 MAIN_PRGRM - 37, 113, 329, 426, 427, 428
 -|/| - File #2 MAIN_PRGRM - 23, 131, 132, 133, 134, 135, 136, 378, 447
 -(L)- File #2 MAIN_PRGRM - 425
 -(U)- File #2 MAIN_PRGRM - 429
 _F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

346

Rung #426

VENT AREA

4 ENABLE

VENT4E

N7:37

9

[425]

VENT SECTION 4

TIMER

VNT4TMR

TON

TIMER ON DELAY

TIMER: T4:248

BASE (SEC): 1.0 (DN)

PRESET: 300

ACCU: 0

T4:248.DN - | | - File #2 MAIN_PRGRM - 608

Rung #427

VENT AREA

4 ENABLE

VENT4E

N7:37

9

[425]

PUMP AREA

4 ENABLE

PUMP4E

N7:38

0

[447]

MANUAL

CONTROL

CLOSE DOOR

8

M-CRCL8

N7:11

2

[3]

MANUAL

CONTROL

CLOSE DOOR

8

M-CRCL8

N7:11

2

[3]

PALLET

DETECTED

LEFT SIDE

BUFFER 3

SEN34

1:037

06

PALLET

DETECTED

RIGHT SIDE

BUFFER 3

SEN36

1:037

10

PALLET

DETECTED

LEFT SIDE

DWELL 5

SEN37

1:037

11

PALLET

DETECTED

RIGHT SIDE

DWELL 5

SEN39

1:037

13

DOOR 8

CLOSED

DRCL8S

1:042

02

DOOR CLOSE

SOLENOID

8 ENABLE

DRCL8

0:045

()

02

MANUAL

CONTROL

CLOSE DOOR

8

M-CRCL8

N7:11

2

[3]

PALLET AT

DOOR 7 AND 8

PLT_DR7,8

83

[421]

MANUAL

DOOR 8

OPEN

MOR8OP

N7:32

(U)

14

[421]

MANUAL

DOOR 8

CLOSE

MOR8CL

N7:32

(L)

2

O:045/02 - | | - File #5 FAULTS - 31

File #6 TECH_RUNGS - 3

-() - File #2 MAIN_PRGRM - 427

N7:32/14 - -(L)- - File #2 MAIN_PRGRM - 49

-(U)- - File #2 MAIN_PRGRM - 427

_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

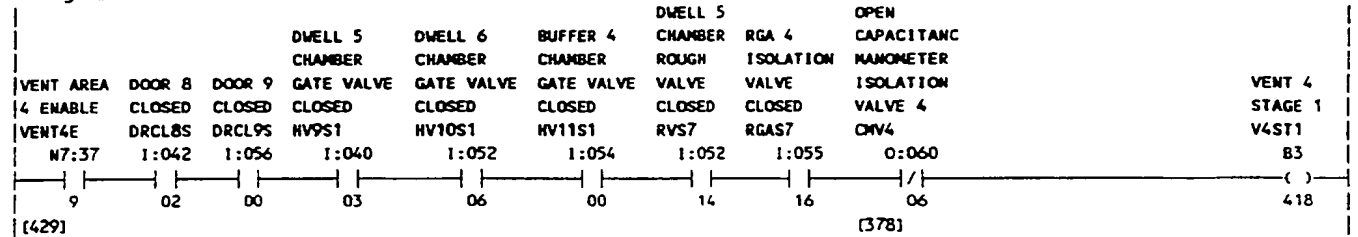
N7:32/2 - -(L)- - File #2 MAIN_PRGRM - 427

-(U)- - File #2 MAIN_PRGRM - 49

_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

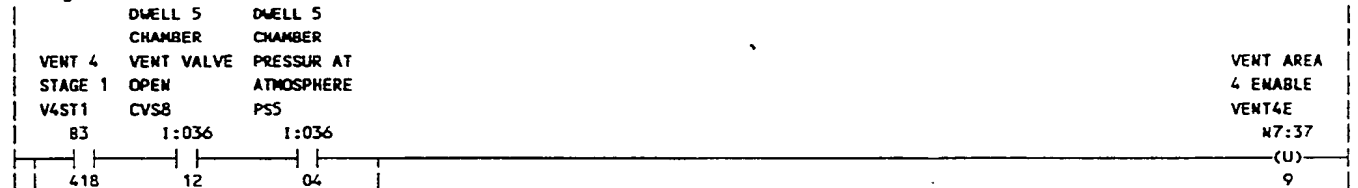
347

Rung #428



83/418 - | | - File #2 MAIN_PRGRM - 402,429
 - () - File #2 MAIN_PRGRM - 428

Rung #429



N7:37/9 - | | - File #2 MAIN_PRGRM - 37, 113, 329, 426, 427, 428
 - | | - File #2 MAIN_PRGRM - 23, 131, 132, 133, 134, 135, 136, 378, 447
 - (L) - File #2 MAIN_PRGRM - 425
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

ABORT SYSTEM

VENT

BORT_SYS_VNT

N7:17

10

[3]

PREPARE FOR

AUTO RUN

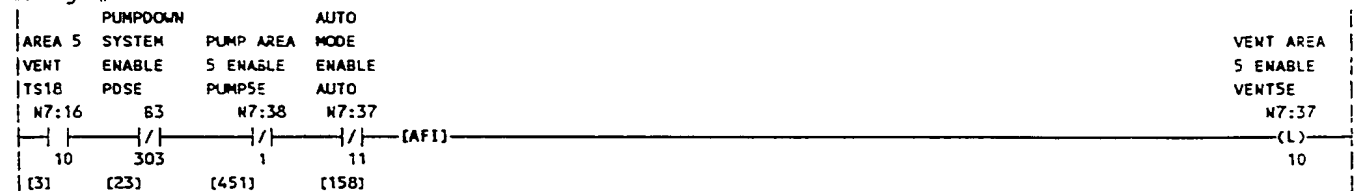
>AUTO

N7:37

1

[162]

Rung #430



N7:37/10 - | | - File #2 MAIN_PRGRM - 114,327,335,431,432,698
 - | | - File #2 MAIN_PRGRM - 23,137,138,451
 - (L) - File #2 MAIN_PRGRM - 430
 - (U) - File #2 MAIN_PRGRM - 433
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #431

VENT AREA
5 ENABLE
VENTSE
N7:37

VENT SECTION 5
TIMER
VNT5THR

TON
TIMER ON DELAY (EW)
TIMER: T4:252
BASE (SEC): 1.0 (DN)
PRESET: 180
ACCUM: 0

T4:252.DN - | | - File #2 MAIH_PRGRM - 608

Rung #432

EXLOCK
CHAMBER EXITLOCK
ROUGH CHAMBER
VENT AREA VALVE GATE VALVE DOOR 10 DOOR 11
5 ENABLE CLOSED CLOSED CLOSED OPEN
VENTSE RVS9 HV12S1 DRCL10S DROP11S
N7:37 I:052 I:054 I:056 I:056
10 16 03 02 05

VENT 5
STAGE 1
VSST1
B3
()
420

B3/420 - | | - File #2 MAIH_PRGRM - 344,351,433

() - File #2 MAIH_PRGRM - 432

Rung #433

EXLOCK
CHAMBER
VENT 5 PRESSUR AT
STAGE 1 ATMOSPHERE
VSST1 PS6
B3 I:052

VENT AREA
5 ENABLE
VENTSE
N7:37

420 04 (U)
10

[432]

N7:37/10 - | | - File #2 MAIH_PRGRM - 114, 327, 335, 431, 432, 698

| / | - File #2 MAIH_PRGRM - 23, 137, 138, 451

-(L) - File #2 MAIH_PRGRM - 430

_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2

ABORT SYSTEM

VENT

BORT_SYS_VNT

N7:17

10

[3]

PREPARE FOR

AUTO RUN

>AUTO

N7:37

1

[162]

Rung #434

HEATER 1 HEATER 2
CHAMBER CHAMBER PIRANI SYSTEM
PUMP AREA GATE VALVE GATE VALVE GUAGE 1 DOOR 2 VENT VENT AREA
1 CLOSE CLOSE NO FAULT OPEN ENABLE 1 ENABLE
TS21 HV1S1 HV2S1 PGNF1 DROP2S SYSVNTE VENT1E
N7:16 I:002 I:004 I:004 I:006 N7:37 N7:37
13 06 00 14 03 5 6

PUMP AREA
1 ENABLE
PUMP1E
N7:37

(L)
13

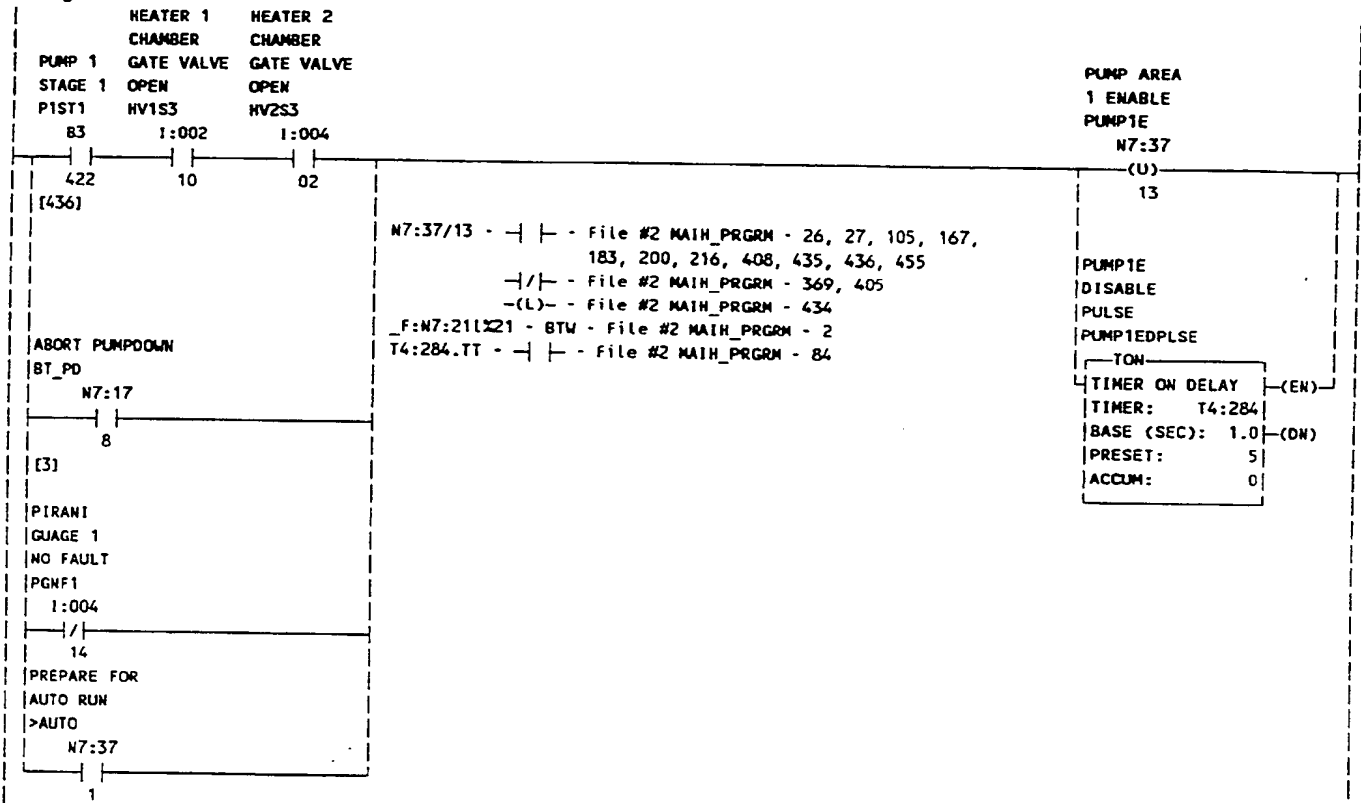
[3]

[369]

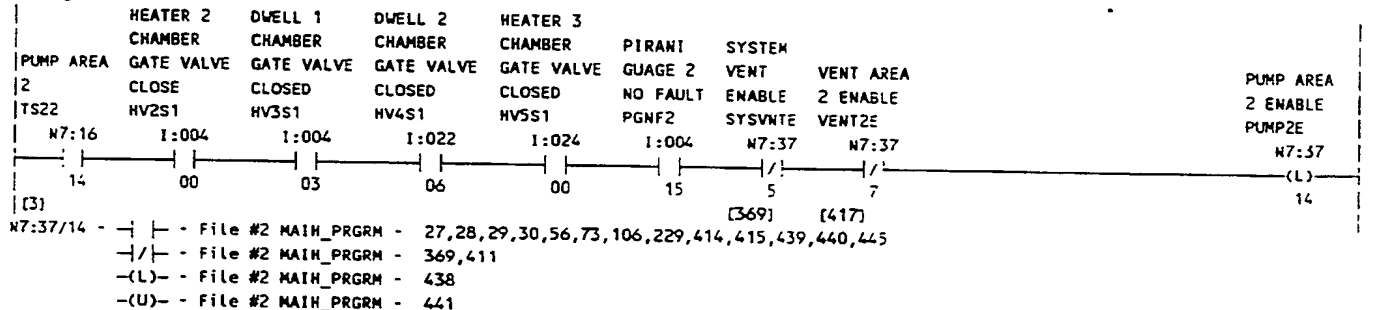
[410]

349

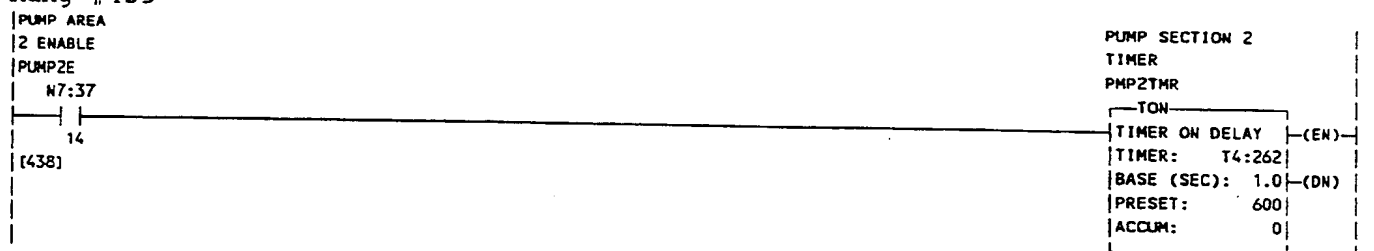
Rung #437



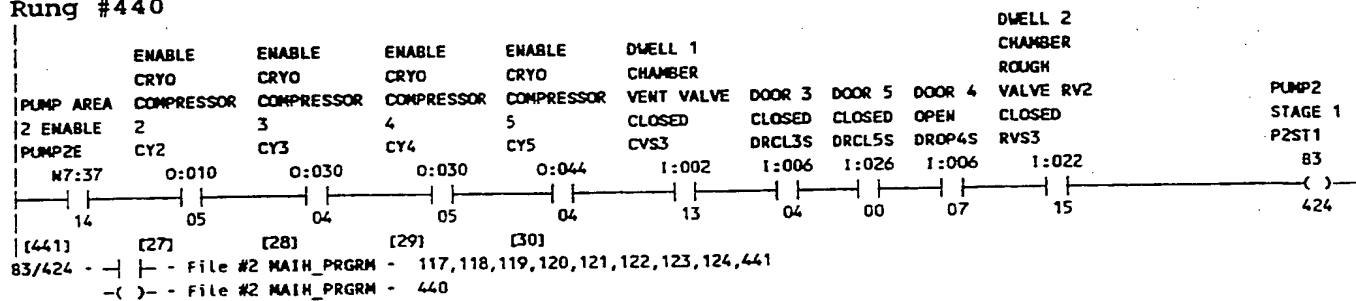
Rung #438



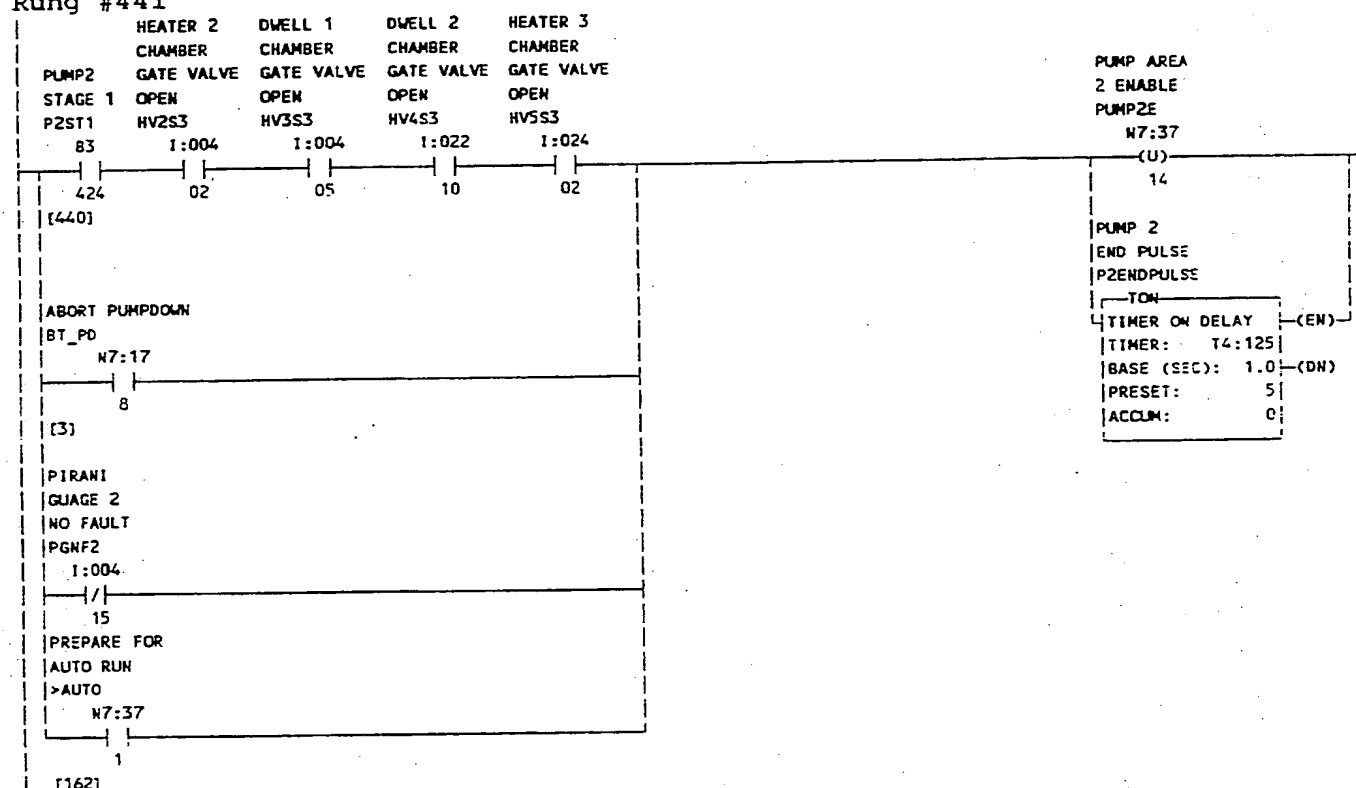
Rung #439



T4:262.DN - | - File #2 MAIN_PRGR. 609
Rung #440



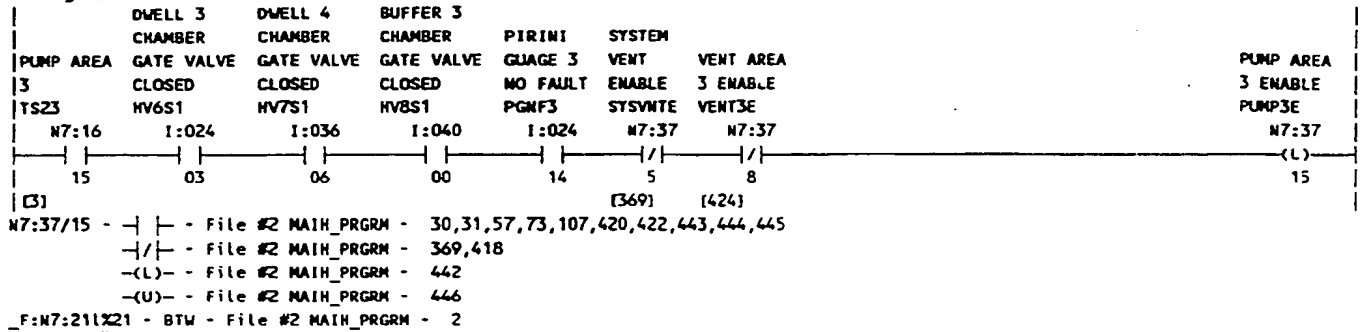
Rung #441



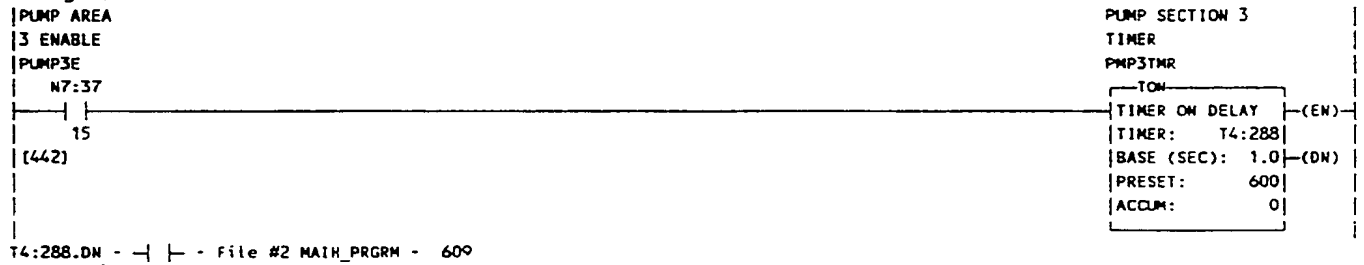
N7:37/14 - | - File #2 MAIN_PRGRM - 27,28,29,30,56,73,106,229,414,415,439,440,445
-|/ - File #2 MAIN_PRGRM - 369,411
-(L) - File #2 MAIN_PRGRM - 438
-(U) - File #2 MAIN_PRGRM - 441
_F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2
T4:125.TT - | - File #2 MAIN_PRGRM - 91

351

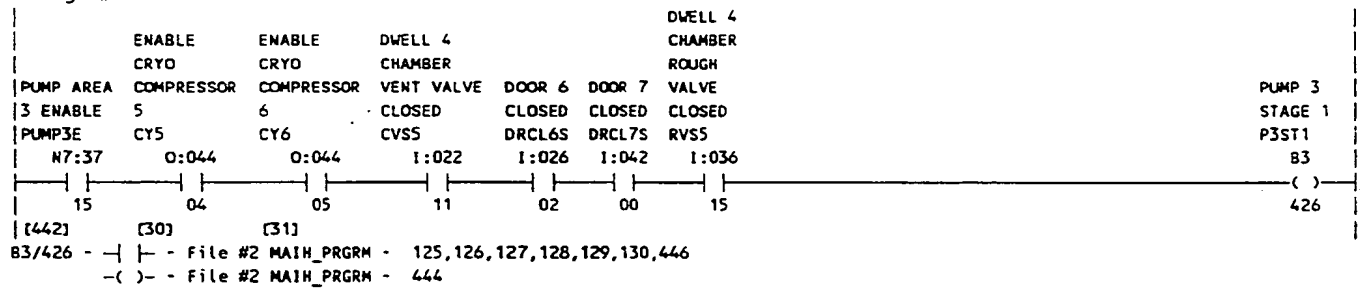
Rung #442



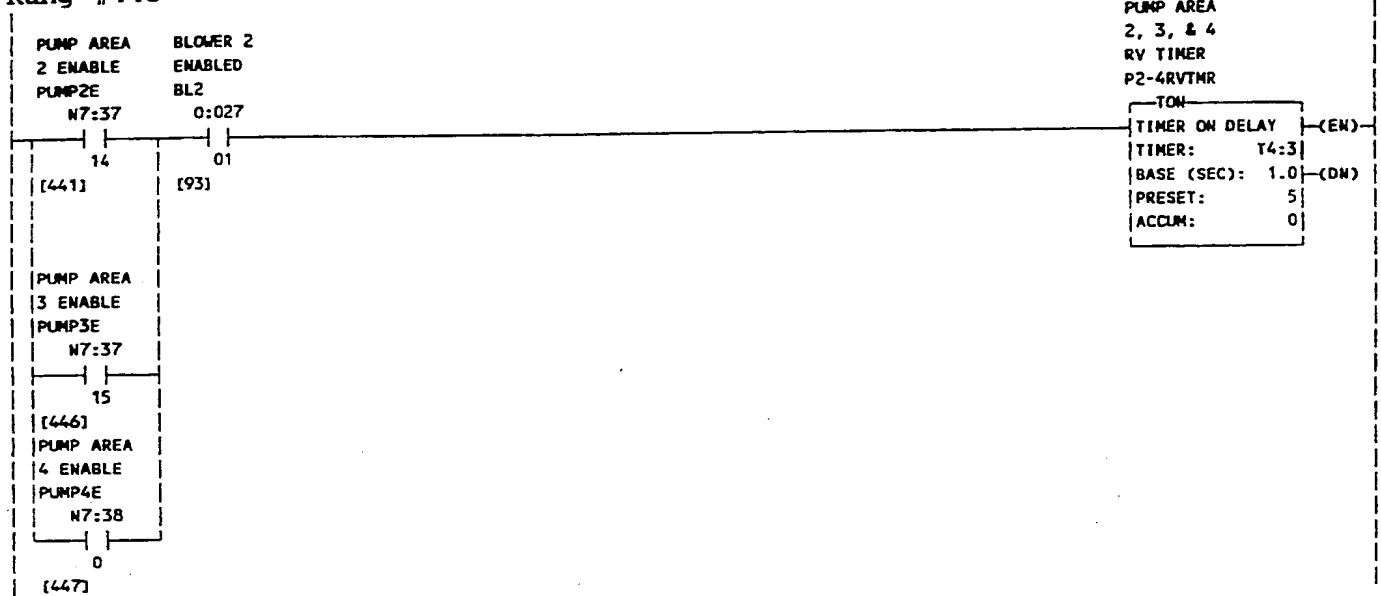
Rung #443



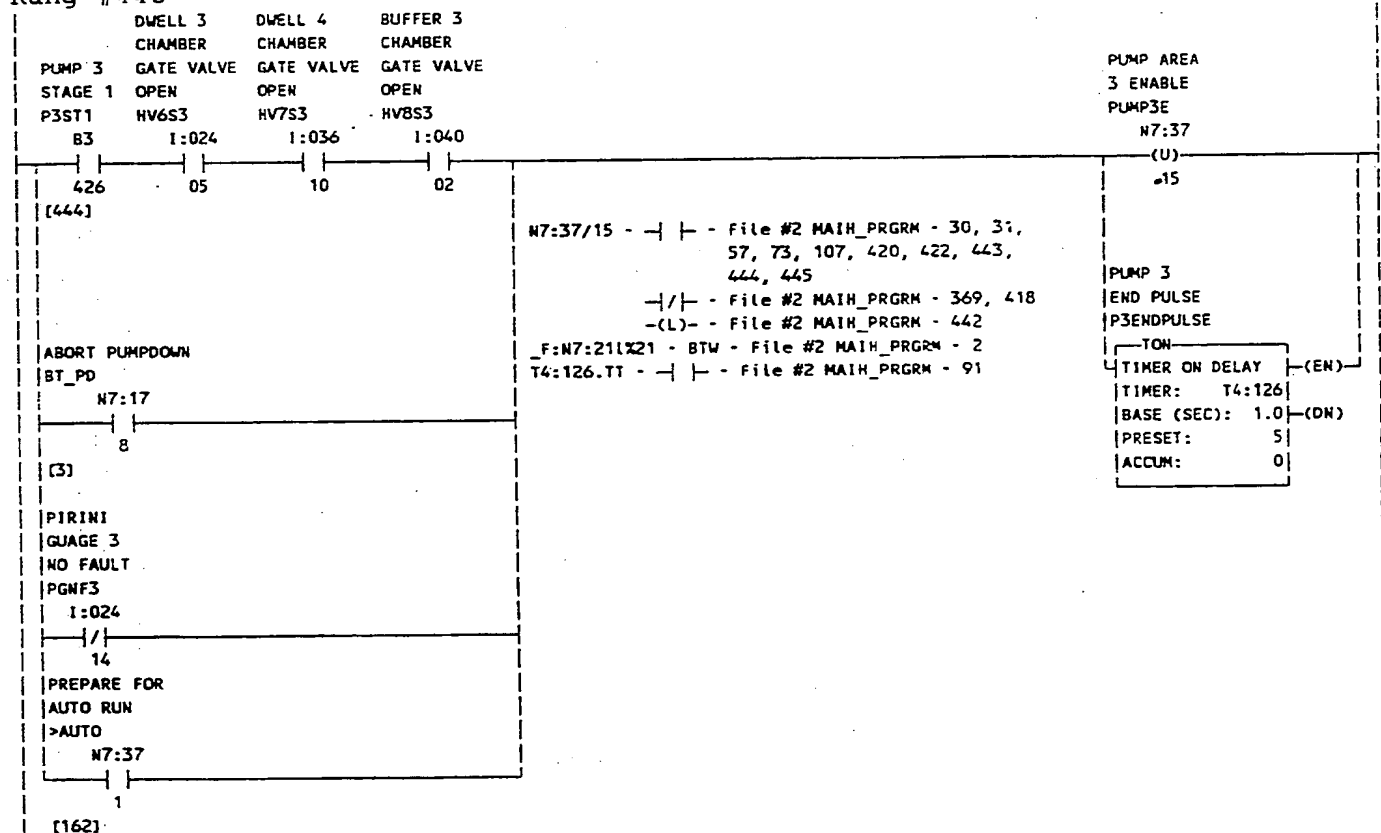
Rung #444



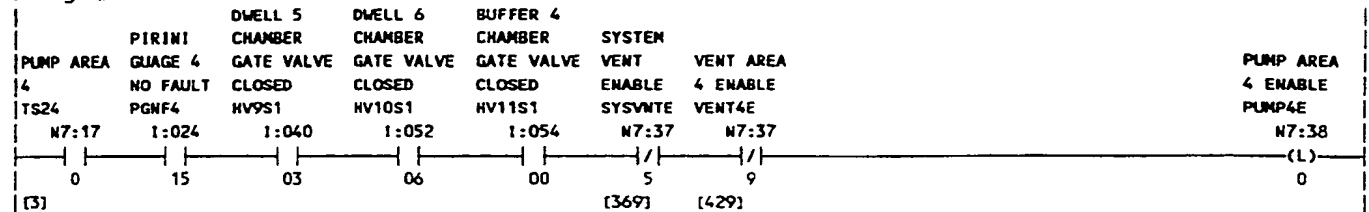
Rung #445



Rung #446



Rung #447



N7:38/0 - | | - File #2 MAIN_PRGRM - 32,33,58,73,108,427,445,448,449
 -|/| - File #2 MAIN_PRGRM - 369,425
 -(L)- File #2 MAIN_PRGRM - 447
 -(U)- File #2 MAIN_PRGRM - 450

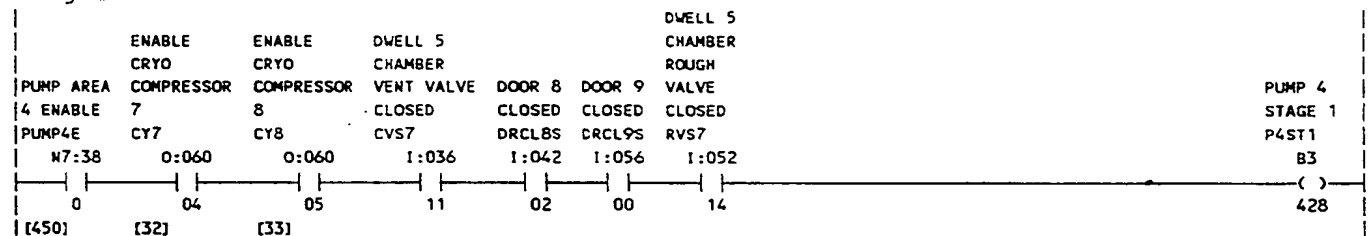
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #448



T4:295.DN - | | - File #2 MAIN_PRGRM - 609

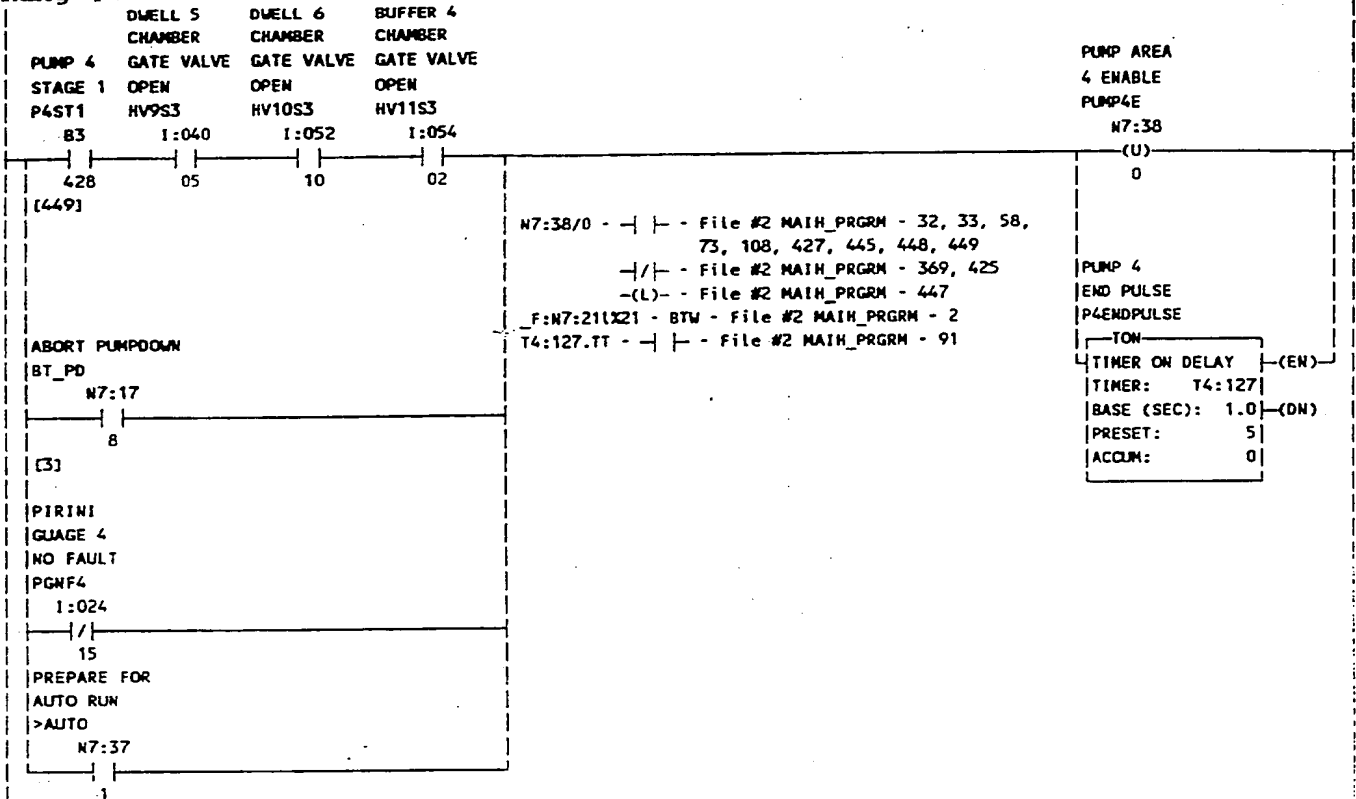
Rung #449



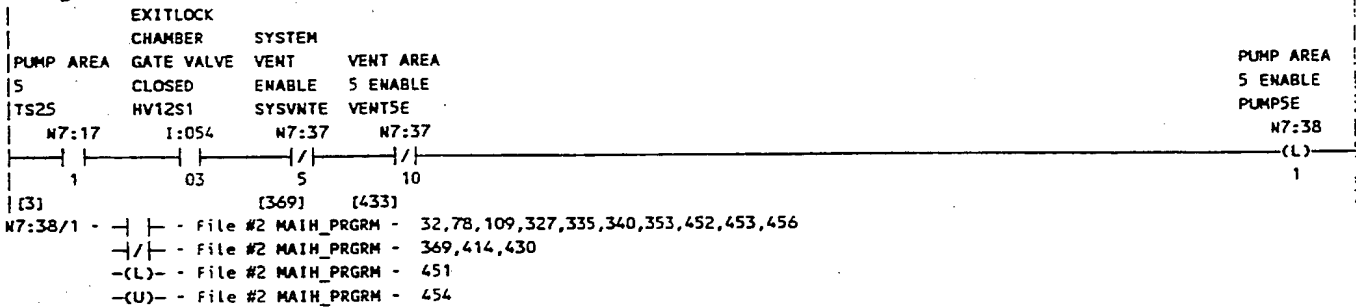
B3/428 - | | - File #2 MAIN_PRGRM - 131,132,133,134,135,136,450
 -() - File #2 MAIN_PRGRM - 449

354

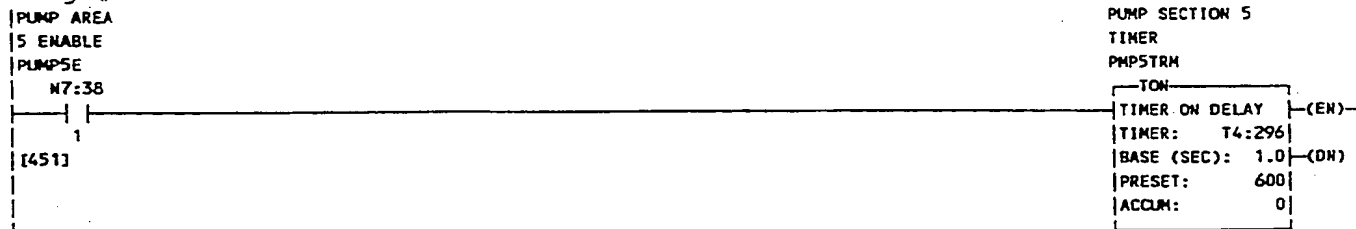
Rung #450



Rung #451



Rung #452



355

T4:296.DM - - - File #2 MAIN_PRGRA. 609

Rung #453

PUMP AREA	ENABLE CRYO	COMPRESSOR	OPEN EXLOCK CHAMBER	DOOR 10	DOOR 11	DOOR 12	PUMP 5
5 ENABLE	7	VENT VALVE	CLOSED	CLOSED	OPEN	CLOSED	STAGE 1
PUMP5E	CY7	CV5	DRCL10S	DROP11S	DRCL12S		P5ST1
W7:38	0:060	0:057	1:056	1:056	1:056		83
1	04	16	02	05	06		430

B3/430 - - File #2 MAIN_PRGRM - 137,138,454

-()- - File #2 MAIN_PRGRM - 453

Rung #454

ABORT PUMPDOWN
BT_PD

N7:17

8

[3]

EXIT
BUFFER

PUMP 5 GATE VALVE
STAGE 1 OPEN

P5ST1 HV12S3

B3 1:054

430 05

[453]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

N7:38/1 - \neg | \neg - File #2 MAIN_PRGRM - 32, 78, 109, 327, 335, 340, 353, 452, 453, 456
 \neg | \neg - File #2 MAIN_PRGRM - 369, 414, 430
-(L)- File #2 MAIN_PRGRM - 451
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
T4:12B.TT - \neg | \neg - File #2 MAIN_PRGRM - 98, 326

PUMP AREA
5 ENABLE
PUMPSE

N7:38

(U)

1

PUMP 5
END PULSE
PSENDPULSE

TON

TIMER ON DELAY (EN)

TIMER: T4:12B

BASE (SEC): 1.0 (DN)

PRESET: 5

ACCUM: 0

[162]

Rung #455

PUMP AREA	BLOWER 1	PUMP AREA	
1 ENABLE	ENABLED	1 RV TIMER	
PUMP1E	BL1	P1RVTHM	
N7:37	Q:007	TON	
13	01	TIMER ON DELAY	(EN)
[437]	[86]	TIMER: T4:2	
		BASE (SEC): 1.0	(DN)
		PRESET: 5	
		ACCUM: 0	

T4:2.DN - -| | - File #2 MAIN_PRGRM - 167

Rung #456

PUMP AREA	BLOWER 3	PUMP AREA
5 ENABLE	ENABLED	5 RV TIMER
PUMPSE	BL3	TSRVTMR
N7:38	O:057	TON
1	01	TIMER ON DELAY (EN)
[454]	[100]	TIMER: T4:4
		BASE (SEC): 1.0 (DN)
		PRESET: 5
		ACCUM: 0

T4:4.DM - -| | - File #2 MAIH_PRGRM 340

Rung #457

MANUAL
CONTROL
CRYO GATE
1 OPEN
M-HV1-1
N7:4

5

[3]

N7:25/5 - -| | - File #2 MAIH_PRGRM - 115
-(U)- - File #2 MAIH_PRGRM - 458
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
N7:26/12 - -(L)- - File #2 MAIH_PRGRM - 458
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL CRYO
GATE 1 OPEN
MCG1OP
N7:25

(L)

5

MANUAL CRYO
GATE 1 CLOSE
MCG1CL
N7:26

(U)

12

Rung #458

MANUAL
CONTROL
CRYO GATE
1 CLOSE
M-HV1-0
N7:5

12

[3]

N7:25/5 - -| | - File #2 MAIH_PRGRM - 115
-(L)- - File #2 MAIH_PRGRM - 457
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
N7:26/12 - -(U)- - File #2 MAIH_PRGRM - 457
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL CRYO
GATE 1 OPEN
MCG1OP
N7:25

(U)

5

MANUAL CRYO
GATE 1 CLOSE
MCG1CL
N7:26

(L)

12

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

COMPRESSOR
1 REGEN-
ERATION
PROGRAM
CYRGH1

83

321

[3:0]

Rung #459

MANUAL
CONTROL
CRYO GATE
Z OPEN
M-HV2-1
N7:4

MANUAL CRYO
GATE 2 OPEN
MCG2OP
N7:25

6

(L)

[3]

N7:25/6 - | | - File #2 MAIN_PRGRM - 117, 118, 462
-(U)- - File #2 MAIN_PRGRM - 460
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:26/13 - -(L)- - File #2 MAIN_PRGRM - 460
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 2 CLOSE
MCG2CL
N7:26
(U)
13

Rung #460

MANUAL
CONTROL
CRYO GATE
Z CLOSE
M-HV2-0
N7:5

MANUAL CRYO
GATE 2 OPEN
MCG2OP
N7:25

13

(U)

[3]

N7:25/6 - | | - File #2 MAIN_PRGRM - 117, 118, 462
-(L)- - File #2 MAIN_PRGRM - 459
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:26/13 - -(U)- - File #2 MAIN_PRGRM - 459
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 2 CLOSE
MCG2CL
N7:26
(L)
13

MANUAL
CONTROL
CRYO GATE
Z THROTTLE
M-HV2-2
N7:5

1

[3]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

COMPRESSOR
Z REGEN-
ERATION
PROGRAM
CYRGW2
B3

322

[3:34]

Rung #461

MANUAL
CONTROL
CRYO GATE
2 THROTTLE
M-HV2-2

N7:5

[3]

N7:26/1 - | | - File #2 MATH_PRGRM - 118,118

-(L)- - File #2 MATH_PRGRM - 461

-(U)- - File #2 MATH_PRGRM - 462

F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MANUAL CRYO
GATE 2 THROTTLE
MCG2TL

N7:26

(L)

1

Rung #462

MANUAL
CONTROL
CRYO GATE
2 CLOSE
M-HV2-0

N7:5

[3]

N7:26/1 - | | - File #2 MATH_PRGRM - 118

-(L)- - File #2 MATH_PRGRM - 461

F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MANUAL CRYO
GATE 2 THROTTLE
MCG2TL

N7:26

(U)

1

MANUAL CRYO
GATE 2 OPEN
MCG2OP

N7:25

6

[460]
PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]
COMPRESSOR
2 REGEN-
ERATION
PROGRAM
CYRGN2

B3

322

[3:34]

Rung #463

MANUAL
CONTROL
CRYO GATE
3 OPEN
M-HV3-1
N7:4

MANUAL CRYO
GATE 3 OPEN
MCG3OP
N7:25

7

[3]

N7:25/7 - | | - File #2 MAIN_PRGRM - 119, 120, 466
-(U)- - File #2 MAIN_PRGRM - 464
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:26/14 - -(L)- - File #2 MAIN_PRGRM - 464
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 3 CLOSE
MCG3CL
N7:26
(U)
14

Rung #464

MANUAL
CONTROL
CRYO GATE
3 CLOSE
M-HV3-0
N7:5

MANUAL CRYO
GATE 3 OPEN
MCG3OP
N7:25

14

[3]

N7:25/7 - | | - File #2 MAIN_PRGRM - 119, 120, 466
-(L)- - File #2 MAIN_PRGRM - 463
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:26/14 - -(U)- - File #2 MAIN_PRGRM - 463
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 3 CLOSE
MCG3CL
N7:26
(L)
14

MANUAL
CONTROL
CRYO GATE
3 THROTTLE
M-HV3-2
N7:5

2

[3]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

[162]
COMPRESSOR
3 REGEN-
ERATION
PROGRAM
CYRGN3
83

323

[3:38]

Rung #465

MANUAL
CONTROL
CRYO GATE
3 THROTTLE
M-HV3-2

N7:5

2

MANUAL CRYO
GATE 3
THROTTLE
MCG3TL

N7:26

(L)
2

[3]

N7:26/2 - | | - File #2 MAIN_PRGRM - 120,120

-(L)- - File #2 MAIN_PRGRM - 465

-(U)- - File #2 MAIN_PRGRM - 466

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #466

MANUAL
CONTROL
CRYO GATE
3 CLOSE
M-HV3-0

N7:5

14

MANUAL CRYO
GATE 3
THROTTLE
MCG3TL

N7:26

(U)
2

[3]

N7:26/2 - | | - File #2 MAIN_PRGRM - 120

-(L)- - File #2 MAIN_PRGRM - 465

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 3 OPEN
MCG3OP

N7:25

7

[464]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
3 REGEN-
ERATION
PROGRAM
CYRGN3

83

323

[3:38]

361

Rung #467

MANUAL
CONTROL
CRYO GATE
4 OPEN
M-HV4-1

N7:4

8

[3]

N7:25/8 - | | - File #2 MAIN_PRGRM - 121, 122, 470
-(U)- - File #2 MAIN_PRGRM - 468
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:26/15 - -(L)- - File #2 MAIN_PRGRM - 468
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 4 OPEN
MCG4OP

N7:25

(L)

8

MANUAL CRYO
GATE 4 CLOSE
MCG4CL

N7:26

(U)

15

Rung #468

MANUAL
CONTROL
CRYO GATE
4 CLOSE
M-HV4-0

N7:5

15

[3]

N7:25/8 - | | - File #2 MAIN_PRGRM - 121, 122, 470
-(L)- - File #2 MAIN_PRGRM - 467
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:26/15 - -(U)- - File #2 MAIN_PRGRM - 467
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CONTROL
CRYO GATE
4 THROTTLE
M-HV4-2

N7:5

3

[3]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGN5

83

325

[3:46]

MANUAL CRYO
GATE 4 OPEN
MCG4OP

N7:25

(U)

8

MANUAL CRYO
GATE 4 CLOSE
MCG4CL

N7:26

(L)

15

362

Rung #469

MANUAL
CONTROL
CRYO GATE
4 THROTTLE
M-HV4-2

N7:5

3

MANUAL CRYO
GATE 4
THROTTLE
MCG4TL

N7:26

(L)

3

[3]

N7:26/3 - | | - File #2 MAIH_PRGRM - 122,122

-(L)- - File #2 MAIH_PRGRM - 469

-(U)- - File #2 MAIH_PRGRM - 470

F:N7:21LX21 - BTW - File #2 MAIH_PRGRM - 2

Rung #470

MANUAL
CONTROL
CRYO GATE
4 CLOSE
M-HV4-0

N7:5

15

MANUAL CRYO
GATE 4
THROTTLE
MCG4TL

N7:26

(U)

3

[3]

N7:26/3 - | | - File #2 MAIH_PRGRM - 122

-(L)- - File #2 MAIH_PRGRM - 469

F:N7:21LX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL CRYO
GATE 4 OPEN
MCG4OP

N7:25

8

[468]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
4 REGEN-
ERATION
PROGRAM
CYRGN4

83

324

[3:42]

Rung #471

MANUAL
CONTROL
CRYO GATE
5 OPEN
M-HV5-1
N7:4

MANUAL CRYO
GATE 5 OPEN
MCG5OP
N7:25

9

(L)
9

[3]

N7:25/9 - | | - File #2 MAIN_PRGRM - 123, 124, 474
-(U)- - File #2 MAIN_PRGRM - 472
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/0 - -(L)- - File #2 MAIN_PRGRM - 472
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 5 CLOSE
MCG5CL
N7:27
(U)
0

Rung #472

MANUAL
CONTROL
CRYO GATE
5 CLOSE
M-HV5-0
N7:6

MANUAL CRYO
GATE 5 OPEN
MCG5OP
N7:25

0

(U)
9

[3]

N7:25/9 - | | - File #2 MAIN_PRGRM - 123, 124, 474
-(L)- - File #2 MAIN_PRGRM - 471
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/0 - -(U)- - File #2 MAIN_PRGRM - 471
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CONTROL
CRYO GATE
5 THROTTLE
M-HV5-2
N7:5

MANUAL CRYO
GATE 5 CLOSE
MCG5CL
N7:27
(L)
0

4

[3]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

COMPRESSOR
4 REGEN-
ERATION
PROGRAM
CYRGN4

83

324

[3:42]

Rung #473

MANUAL
CONTROL
CRYO GATE
5 THROTTLE
M-HVS-2

N7:5

4

MANUAL CRYO
GATE 5
THROTTLE
MCGSTL

N7:26

(L)

4

[3]

N7:26/4 - | | - File #2 MAIN_PRGRM - 124,124

-(L)- - File #2 MAIN_PRGRM - 473

-(U)- - File #2 MAIN_PRGRM - 474

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #474

MANUAL
CONTROL
CRYO GATE
5 CLOSE
M-HVS-0

N7:6

0

MANUAL CRYO
GATE 5
THROTTLE
MCGSTL

N7:26

(U)

4

[3]

N7:26/4 - | | - File #2 MAIN_PRGRM - 124

-(L)- - File #2 MAIN_PRGRM - 473

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 5 OPEN
MCGSOP

N7:25

9

[472]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
4 REGEN-
ERATION
PROGRAM
CYRGN4

83

324

[3:42]

Rung #475

MANUAL
CONTROL
CRYO GATE
6 OPEN
M-HV6-1
N7:4

MANUAL CRYO
GATE 6 OPEN
MCG6OP
N7:25

10

(L)
10

[3]

N7:25/10 - | | - File #2 MAIN_PRGRM - 125, 126, 478
-(U)- - File #2 MAIN_PRGRM - 476
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/1 - -(L)- - File #2 MAIN_PRGRM - 476
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 6 CLOSE
MCG6CL
N7:27
(U)
1

Rung #476

MANUAL
CONTROL
CRYO GATE
6 CLOSE
M-HV6-0
N7:6

MANUAL CRYO
GATE 6 OPEN
MCG6OP
N7:25

1

(U)
10

[3]

N7:25/10 - | | - File #2 MAIN_PRGRM - 125, 126, 478
-(L)- - File #2 MAIN_PRGRM - 475
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/1 - -(U)- - File #2 MAIN_PRGRM - 475
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 6 CLOSE
MCG6CL
N7:27
(L)
1

MANUAL
CONTROL
CRYO GATE
6 THROTTLE
M-HV6-2
N7:5

5

[3]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGMS
83

325

[3:46]

Rung #477

MANUAL
CONTROL
CRYO GATE
6 THROTTLE
M-HV6-2

MANUAL CRYO
GATE 6
THROTTLE
MCG6TL

N7:5

N7:26

(L)

5

5

[3]

N7:26/5 - | | - File #2 MAIN_PRGRM - 126,126

-(L)- - File #2 MAIN_PRGRM - 477

-(U)- - File #2 MAIN_PRGRM - 478

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #478

MANUAL
CONTROL
CRYO GATE
6 CLOSE
M-HV6-0

MANUAL CRYO
GATE 6
THROTTLE
MCG6TL

N7:6

N7:26

(U)

1

5

[3]

N7:26/5 - | | - File #2 MAIN_PRGRM - 126

-(L)- - File #2 MAIN_PRGRM - 477

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 6 OPEN
MCG6OP

N7:25

10

[476]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]
COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGN5

E3

325

[3:46]

Rung #479

MANUAL
CONTROL
CRYO GATE
7 OPEN
M-HV7-1
N7:4

MANUAL CRYO
GATE 7 OPEN
MCG7OP
N7:25

11
[3]
N7:25/11 - | | - File #2 MAIH_PRGRM - 127, 128, 482
-(U)- - File #2 MAIH_PRGRM - 480
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
N7:27/2 - -(L)- - File #2 MAIH_PRGRM - 480
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2

(L)
11
MANUAL CRYO
GATE 7 CLOSE
MCG7CL
N7:27
(U)
2

Rung #480

MANUAL
CONTROL
CRYO GATE
7 CLOSE
M-HV7-0
N7:6

MANUAL CRYO
GATE 7 OPEN
MCG7OP
N7:25

2
[3]
N7:25/11 - | | - File #2 MAIH_PRGRM - 127, 128, 482
-(L)- - File #2 MAIH_PRGRM - 479
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2
N7:27/2 - -(U)- - File #2 MAIH_PRGRM - 479
_F:N7:211X21 - BTW - File #2 MAIH_PRGRM - 2

(U)
11
MANUAL CRYO
GATE 7 CLOSE
MCG7CL
N7:27
(L)
2

MANUAL
CONTROL
CRYO GATE
7 THROTTLE
M-HV7-2
N7:5

6
[3]
PREPARE FOR
AUTO RUN
>AUTO
N7:37

1
[162]
COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGN5
83

325
[3:46]

Rung #481

MANUAL
CONTROL
CRYO GATE
7 THROTTLE
M-HV7-2

MANUAL CRYO
GATE 7
THROTTLE
MCG7TL

N7:5
6
N7:26
(L)
6

[3]
N7:26/6 - | | - File #2 MAIN_PRGRM - 128,128
-(L)- - File #2 MAIN_PRGRM - 481
-(U)- - File #2 MAIN_PRGRM - 482
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #482

MANUAL
CONTROL
CRYO GATE
7 CLOSE
M-HV7-0

MANUAL CRYO
GATE 7
THROTTLE
MCG7TL

N7:6
2
N7:26
(U)
6

[3]
N7:26/6 - | | - File #2 MAIN_PRGRM - 128
-(L)- - File #2 MAIN_PRGRM - 481
F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 7 OPEN
MCG7OP

N7:25

11
[480]
PREPARE FOR
AUTO RUN
>AUTO

N7:37

1
[162]
COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGNS

83

325
[3:46]

Rung #483

MANUAL
CONTROL
CRYO GATE
8 OPEN
M-HVB-1
N7:4

MANUAL CRYO
GATE 8 OPEN
HCG8OP
N7:25

12

(L)

[3]

12

N7:25/12 - | | - File #2 MAIN_PRGRM - 129, 130, 486
-(U)- - File #2 MAIN_PRGRM - 484
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/3 - -(L)- - File #2 MAIN_PRGRM - 484
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 8 CLOSE
HCG8CL
N7:27
(U)

3

Rung #484

MANUAL
CONTROL
CRYO GATE
8 CLOSE
M-HVB-0
N7:6

MANUAL CRYO
GATE 8 OPEN
HCG8OP
N7:25

3

(U)

[3]

12

N7:25/12 - | | - File #2 MAIN_PRGRM - 129, 130, 486
-(L)- - File #2 MAIN_PRGRM - 483
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/3 - -(U)- - File #2 MAIN_PRGRM - 483
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CONTROL
CRYO GATE
8 THROTTLE
M-HVB-2
N7:5

MANUAL CRYO
GATE 8 CLOSE
HCG8CL
N7:27
(L)

3

7

[3]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

COMPRESSOR
6 REGEN-
ERATION
PROGRAM
CYRGN6

83

326

[3:52]

Rung #485

MANUAL
CONTROL
CRYO GATE
8 THROTTLE
M-MVB-2

N7:5

7

MANUAL CRYO
GATE 8
THROTTLE
MCG8TL

N7:26

(L)
7

[3]

N7:26/7 - | | - File #2 MAIN_PRGRM - 130,130

-(L)- - File #2 MAIN_PRGRM - 485

-(U)- - File #2 MAIN_PRGRM - 486

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #486

MANUAL
CONTROL
CRYO GATE
8 CLOSE
M-MVB-0

N7:6

3

MANUAL CRYO
GATE 8
THROTTLE
MCG8TL

N7:26

(U)
7

[3]

N7:26/7 - | | - File #2 MAIN_PRGRM - 130

-(L)- - File #2 MAIN_PRGRM - 485

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 8 OPEN
MCG8OP

N7:25

12

[484]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
6 REGEN-
ERATION
PROGRAM
CYRGN6

63

326

[3:52]

Rung #487

MANUAL
CONTROL
CRYO GATE
9 OPEN
M-HV9-1
N7:4

MANUAL CRYO
GATE 9 OPEN
MCG9OP
N7:25

13

(L)
13

(3)
N7:25/13 - | | - File #2 MAIH_PRGRM - 131, 132, 490
-(U)- - File #2 MAIH_PRGRM - 488
_F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2
N7:27/4 - -(L)- - File #2 MAIH_PRGRM - 488
_F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL CRYO
GATE 9 CLOSE
MCG9CL
N7:27
(U)
4

Rung #488

MANUAL
CONTROL
CRYO GATE
9 CLOSE
M-HV9-0
N7:6

MANUAL CRYO
GATE 9 OPEN
MCG9OP
N7:25

4

(U)
13

(3)
N7:25/13 - | | - File #2 MAIH_PRGRM - 131, 132, 490
-(L)- - File #2 MAIH_PRGRM - 487
_F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2
N7:27/4 - -(U)- - File #2 MAIH_PRGRM - 487
_F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL
CONTROL
CRYO GATE
9 THROTTLE
M-HV9-2
N7:5

MANUAL CRYO
GATE 9 CLOSE
MCG9CL
N7:27
(L)
4

8

(3)
PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

(162)
COMPRESSOR
7 REGEN-
ERATION
PROGRAM
CYRGN7
63

327

(3:57)

Rung #489

MANUAL
CONTROL
CRYO GATE
9 THROTTLE

M-HV9-2
N7:5

8

MANUAL CRYO
GATE 9
THROTTLE
MCG9TL

N7:26

(L)

8

[3]

N7:26/8 - | | - File #2 MAIN_PRGRM - 132,132

-(L)- - File #2 MAIN_PRGRM - 489

-(U)- - File #2 MAIN_PRGRM - 490

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #490

MANUAL
CONTROL
CRYO GATE
9 CLOSE
M-HV9-0

N7:6

4

MANUAL CRYO
GATE 9
THROTTLE
MCG9TL

N7:26

(U)

8

[3]

N7:26/8 - | | - File #2 MAIN_PRGRM - 132

-(L)- - File #2 MAIN_PRGRM - 489

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 9 OPEN
MCG9OP

N7:25

13

[488]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
7 REGEN-
ERATION
PROGRAM
CYRGN7

83

327

[3:57]

Rung #582

MOTOR 15

REVERSE

ENABLE

M15RE

N7:19

14

[3]

B3/115 - | | - File #2 MAIN_PRGRM - 297
 -|/| - File #2 MAIN_PRGRM - 295
 -(U)- - File #2 MAIN_PRGRM - 601
 N7:40/14 - -(U)- - File #2 MAIN_PRGRM - 601
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/11 - -(L)- - File #2 MAIN_PRGRM - 601
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 15

REVERSE

M15R

83

-(L)-

115

MANUAL

MOTOR 15

REVERSE

ENABLE

M15RE

N7:40

-(L)-

14

MANUAL

MOTOR 15

REVERSE

DISABLE

M15RD

N7:35

-(U)-

11

Rung #583

MOTOR 16

REVERSE

ENABLE

M16RE

N7:19

15

[3]

B3/116 - | | - File #2 MAIN_PRGRM - 306
 -|/| - File #2 MAIN_PRGRM - 306
 -(U)- - File #2 MAIN_PRGRM - 602
 N7:40/15 - -(U)- - File #2 MAIN_PRGRM - 602
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/12 - -(L)- - File #2 MAIN_PRGRM - 602
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 16

REVERSE

M16R

83

-(L)-

116

MANUAL

MOTOR 16

REVERSE

ENABLE

M16RE

N7:40

-(L)-

15

MANUAL

MOTOR 16

REVERSE

DISABLE

M16RD

N7:35

-(U)-

12

374

Rung #584

MOTOR 17
REVERSE
ENABLE
M17RE
N7:20

0

[3]

83/117 - | | - File #2 MAIN_PRGRM - 312
 - | | - File #2 MAIN_PRGRM - 310
 -(U)- - File #2 MAIN_PRGRM - 603
 N7:41/0 - -(U)- - File #2 MAIN_PRGRM - 603
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/13 - -(L)- - File #2 MAIN_PRGRM - 603
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 17
REVERSE
M17R

83

(L)

117

MANUAL
MOTOR 17
REVERSE
ENABLE
M17RE
N7:41

(L)

0

MANUAL
MOTOR 17
REVERSE
DISABLE
M17RD
N7:35

(U)

13

Rung #585

MOTOR 18
REVERSE
ENABLE
M18RE
N7:20

1

[3]

83/118 - | | - File #2 MAIN_PRGRM - 317
 - | | - File #2 MAIN_PRGRM - 315
 -(U)- - File #2 MAIN_PRGRM - 604
 N7:41/1 - -(U)- - File #2 MAIN_PRGRM - 604
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/14 - -(L)- - File #2 MAIN_PRGRM - 604
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 18
REVERSE
M18R

83

(L)

118

MANUAL
MOTOR 18
REVERSE
ENABLE
M18RE
N7:41

(L)

1

MANUAL
MOTOR 18
REVERSE
DISABLE
M18RD
N7:35

(U)

14

Rung #586

MOTOR 19
REVERSE
ENABLE
M19RE

N7:20

2

(3)

83/119 - | | - File #2 MAIN_PRGRM - 322
 -|/| - File #2 MAIN_PRGRM - 320
 -(U)- - File #2 MAIN_PRGRM - 605
 N7:41/2 - -(U)- - File #2 MAIN_PRGRM - 605
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/15 - -(L)- - File #2 MAIN_PRGRM - 605
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 19
REVERSE
M19R

83

(L)

119

MANUAL
MOTOR 19
REVERSE
ENABLE
M19RE
N7:41

(L)

2

MANUAL
MOTOR 19
REVERSE
DISABLE
M19RD
N7:35

(U)

15

Rung #587

MOTOR 20
REVERSE
ENABLE
M20RE

N7:20

3

(3)

83/120 - | | - File #2 MAIN_PRGRM - 333
 -|/| - File #2 MAIN_PRGRM - 331
 -(U)- - File #2 MAIN_PRGRM - 606
 N7:41/3 - -(U)- - File #2 MAIN_PRGRM - 606
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:36/0 - -(L)- - File #2 MAIN_PRGRM - 606
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 20
REVERSE
M20R

83

(L)

120

MANUAL
MOTOR 20
REVERSE
ENABLE
M20RE
N7:41

(L)

3

MANUAL
MOTOR 20
REVERSE
DISABLE
M20RD
N7:36

(U)

0

Rung #588

MOTOR 21
REVERSE
ENABLE
M21RE
N7:20

4
[3]

B3/121 - | | - File #2 MAIN_PRGRM - 357
-|/| - File #2 MAIN_PRGRM - 355
-(U)- - File #2 MAIN_PRGRM - 607
N7:41/4 - -(U)- - File #2 MAIN_PRGRM - 607
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:36/1 - -(L)- - File #2 MAIN_PRGRM - 607
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 21
REVERSE
M21R

83
(L)
121

MANUAL
MOTOR 21
REVERSE
ENABLE
M21_RE
N7:41

(L)
4

MANUAL
MOTOR 21
REVERSE
DISABLE
M21RD
N7:36

(U)
1

Rung #589

MOTOR 3
REVERSE
DISABLE
M3RD
N7:13

15
[3]

B3/103 - | | - File #2 MAIN_PRGRM - 187
-|/| - File #2 MAIN_PRGRM - 185
-(L)- - File #2 MAIN_PRGRM - 570
N7:40/2 - -(L)- - File #2 MAIN_PRGRM - 570
PREPARE FOR _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
AUTO RUN N7:34/15 - -(U)- - File #2 MAIN_PRGRM - 570
>AUTO _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:37

1
[162]

MOTOR 3
REVERSE
M3R

83
(U)
103

MANUAL
MOTOR 3
REVERSE
ENABLE
M3RE
N7:40

(U)
2

MANUAL
MOTOR 3
REVERSE
DISABLE
M3RD
N7:34

(L)
15

Rung #590

MOTOR 4
REVERSE
DISABLE
M4RD

N7:14

0
[3]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1
[162]

B3/104 - | | - File #2 MAIN_PRGRM - 192
 - | | - File #2 MAIN_PRGRM - 190
 -(L)- - File #2 MAIN_PRGRM - 571
 N7:40/3 - -(L)- - File #2 MAIN_PRGRM - 571
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/0 - -(U)- - File #2 MAIN_PRGRM - 571
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 4
REVERSE
M4R

B3

(U)
104

MANUAL
MOTOR 4
REVERSE
ENABLE

M4RE

N7:40

(U)
3

MANUAL
MOTOR 4
REVERSE
DISABLE
M4RD

N7:35

(L)
0

Rung #591

MOTOR 5
REVERSE
DISABLE
M5RD

N7:14

1
[3]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1
[162]

B3/105 - | | - File #2 MAIN_PRGRM - 197
 - | | - File #2 MAIN_PRGRM - 195
 -(L)- - File #2 MAIN_PRGRM - 572
 N7:40/4 - -(L)- - File #2 MAIN_PRGRM - 572
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/1 - -(U)- - File #2 MAIN_PRGRM - 572
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 5
REVERSE
M5R

B3

(U)
105

MANUAL
MOTOR 5
REVERSE
ENABLE

M5RE

N7:40

(U)
4

MANUAL
MOTOR 5
REVERSE
DISABLE
M5RD

N7:35

(L)
1

Rung #592

MOTOR 6
REVERSE
DISABLE
M6RD

N7:14

2

[3]

B3/106 - \neg | \neg - File #2 MAIN_PRGRM - 220
 \neg | \neg - File #2 MAIN_PRGRM - 218
 \neg (L)- - File #2 MAIN_PRGRM - 573
N7:40/5 - \neg (L)- - File #2 MAIN_PRGRM - 573
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:35/2 - \neg (U)- - File #2 MAIN_PRGRM - 573
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

MOTOR 6
REVERSE
M6R

83

(U)

106

MANUAL
MOTOR 6
REVERSE
ENABLE

MM6RE
N7:40

(U)

5

MANUAL
MOTOR 6
REVERSE
DISABLE
MM6RD

N7:35

(L)

2

Rung #593

MOTOR 7
REVERSE
DISABLE
M7RD

N7:14

3

[3]

B3/107 - \neg | \neg - File #2 MAIN_PRGRM - 233
 \neg | \neg - File #2 MAIN_PRGRM - 231
 \neg (L)- - File #2 MAIN_PRGRM - 574
N7:40/6 - \neg (L)- - File #2 MAIN_PRGRM - 574
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:35/3 - \neg (U)- - File #2 MAIN_PRGRM - 574
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

MOTOR 7
REVERSE
M7R

83

(U)

107

MANUAL
MOTOR 7
REVERSE
ENABLE
MM7RE

N7:40

(U)

6

MANUAL
MOTOR 7
REVERSE
DISABLE
MM7RD

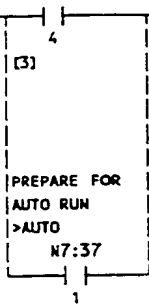
N7:35

(L)

3

Rung #594

MOTOR 8
REVERSE
DISABLE
M8RD
N7:14



[162]

B3/108 - | | - File #2 MAIN_PRGRM - 249
- | | - File #2 MAIN_PRGRM - 249
-(L)- - File #2 MAIN_PRGRM - 575
N7:40/7 - -(L)- - File #2 MAIN_PRGRM - 575
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:35/4 - -(U)- - File #2 MAIN_PRGRM - 575
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 8
REVERSE
M8R

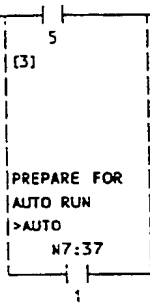
B3
(U)
108

MANUAL
MOTOR 8
REVERSE
ENABLE
M8BRE
N7:40
(U)
7

MANUAL
MOTOR 8
REVERSE
DISABLE
M8RD
N7:35
(L)
4

Rung #595

MOTOR 9
REVERSE
DISABLE
M9RD
N7:14



[162]

B3/109 - | | - File #2 MAIN_PRGRM - 255
- | | - File #2 MAIN_PRGRM - 253
-(L)- - File #2 MAIN_PRGRM - 576
N7:40/8 - -(L)- - File #2 MAIN_PRGRM - 576
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:35/5 - -(U)- - File #2 MAIN_PRGRM - 576
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

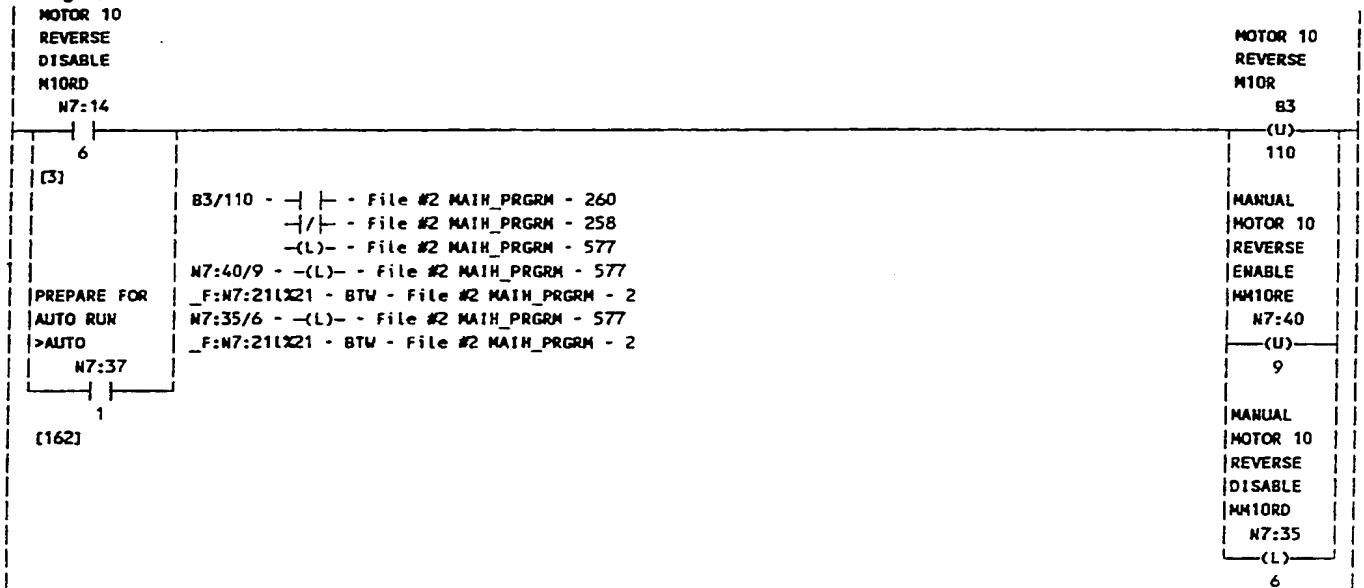
MOTOR 9
REVERSE
M9R

B3
(U)
109

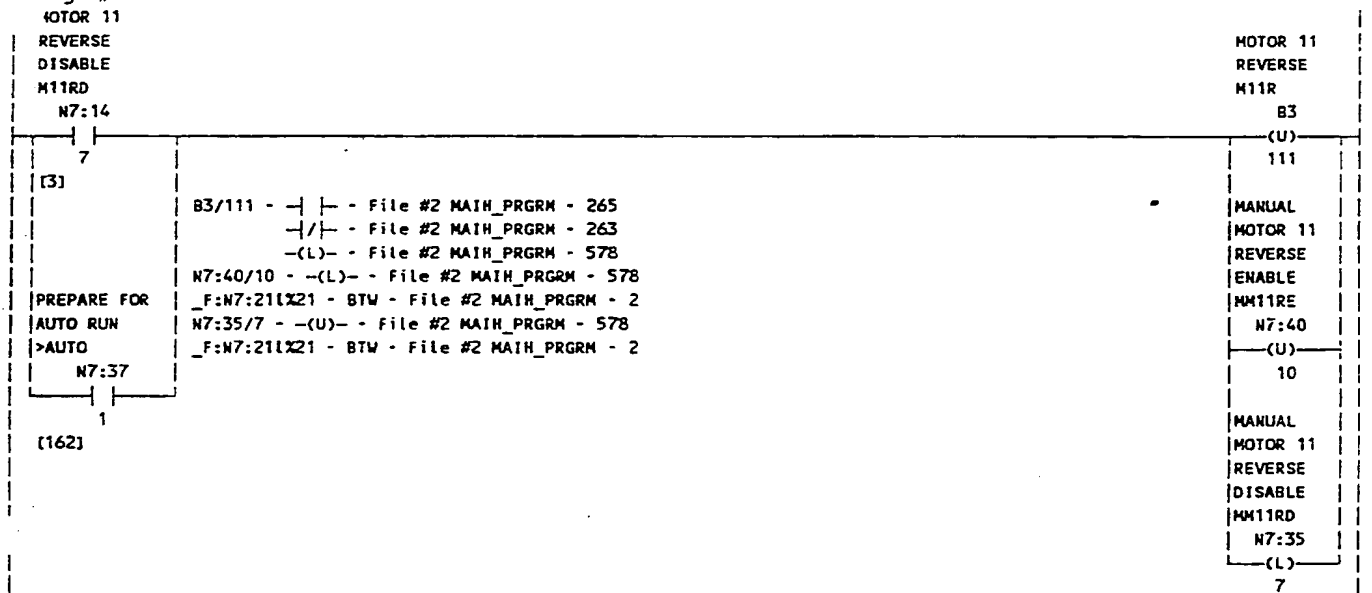
MANUAL
MOTOR 9
REVERSE
ENABLE
M9BRE
N7:40
(U)
8

MANUAL
MOTOR 9
REVERSE
DISABLE
M9RD
N7:35
(L)
5

Rung #596



Rung #597



Rung #598

MOTOR 12
REVERSE
DISABLE
M12RD
N7:14

MOTOR 12
REVERSE
M12R

83

(U)

112

[3]

B3/112 - | | - File #2 MAIN_PRGRM - 281
 -|/| - File #2 MAIN_PRGRM - 281
 -(L)- - File #2 MAIN_PRGRM - 579
 N7:40/11 - -(L)- - File #2 MAIN_PRGRM - 579
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/8 - -(U)- - File #2 MAIN_PRGRM - 579
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

MANUAL
MOTOR 12
REVERSE
ENABLE
MM12RE
N7:40

(U)

11

MANUAL
MOTOR 12
REVERSE
DISABLE
MM12RD
N7:35

(L)

8

Rung #599

MOTOR 13
REVERSE
DISABLE
M13RD
N7:14

MOTOR 13
REVERSE
M13R

83

(U)

113

[3]

B3/113 - | | - File #2 MAIN_PRGRM - 287
 -|/| - File #2 MAIN_PRGRM - 285
 -(L)- - File #2 MAIN_PRGRM - 580
 N7:40/12 - -(L)- - File #2 MAIN_PRGRM - 580
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/9 - -(U)- - File #2 MAIN_PRGRM - 580
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

MANUAL
MOTOR 13
REVERSE
ENABLE
MM13RE
N7:40

(U)

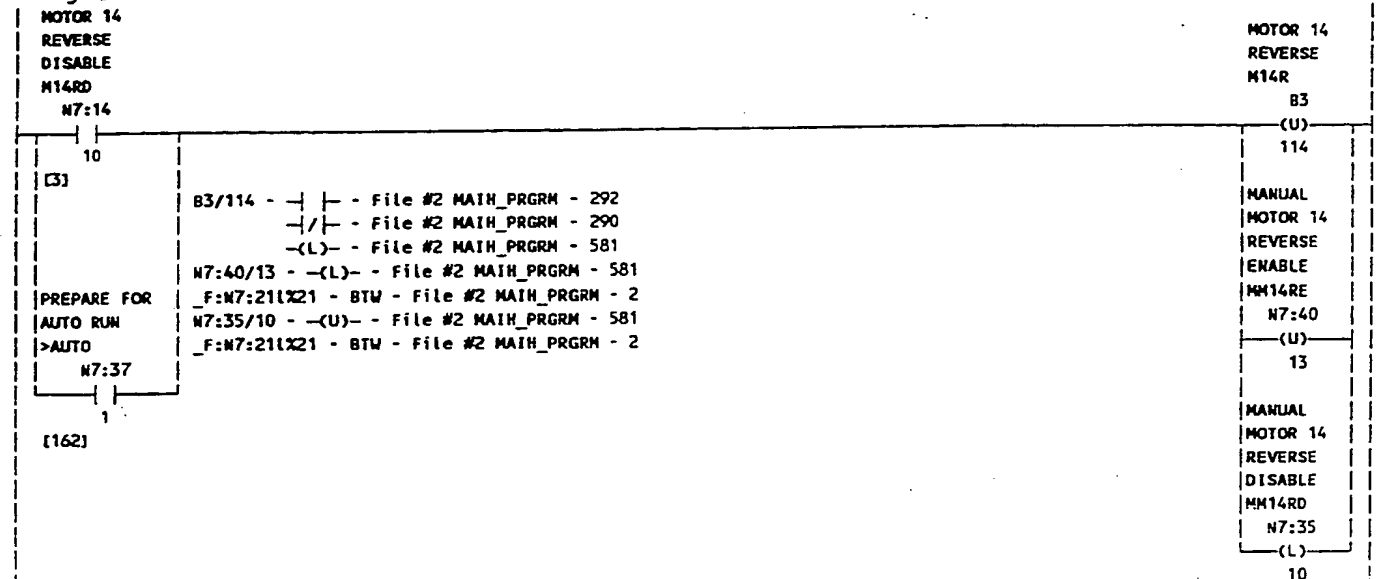
12

MANUAL
MOTOR 13
REVERSE
DISABLE
MM13RD
N7:35

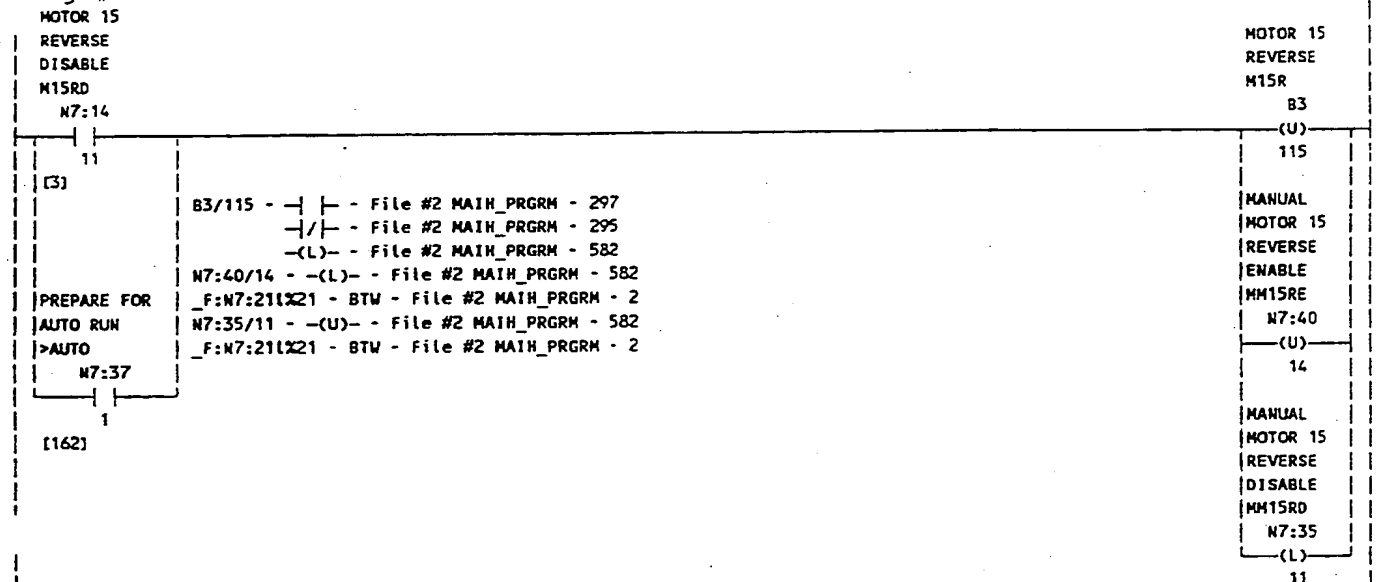
(L)

9

Rung #600

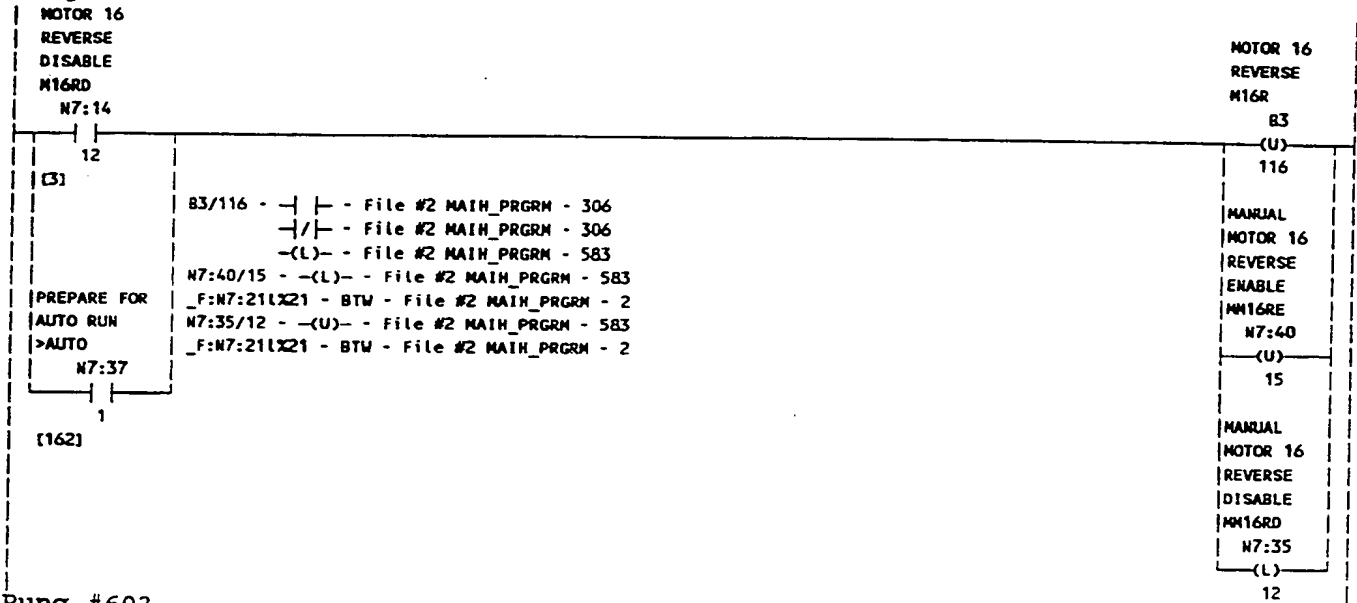


Rung #601

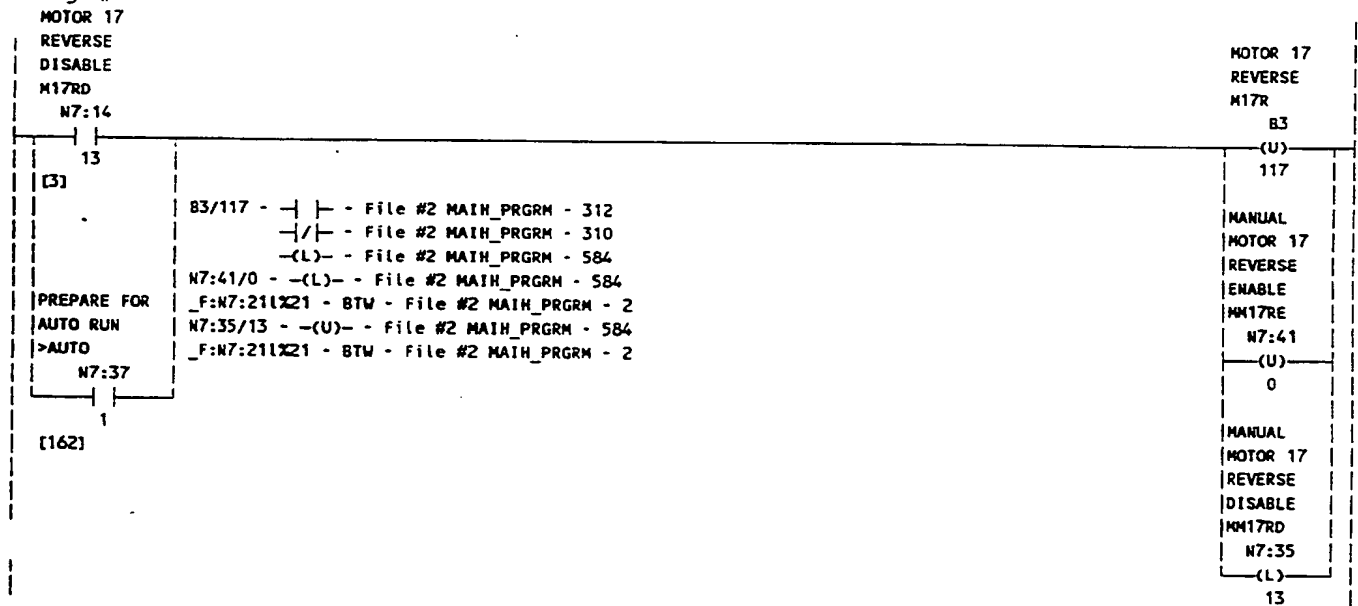


383

Rung #602



Rung #603



384

Rung #604

MOTOR 18
REVERSE
DISABLE
M18RD

N7:14

14

[3]

B3/118 - | | - File #2 MAIN_PRGRM - 317
 -|/| - File #2 MAIN_PRGRM - 315
 -(L)- - File #2 MAIN_PRGRM - 585
 N7:41/1 - -(L)- - File #2 MAIN_PRGRM - 585
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/14 - -(U)- - File #2 MAIN_PRGRM - 585
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

MOTOR 18
REVERSE
M18R

83

(U)

118

MANUAL
MOTOR 18
REVERSE
ENABLE
M18RE

N7:41

(U)

1

MANUAL
MOTOR 18
REVERSE
DISABLE
M18RD

N7:35

(L)

14

Rung #605

MOTOR 19
REVERSE
DISABLE
M19RD

N7:14

15

[3]

B3/119 - | | - File #2 MAIN_PRGRM - 322
 -|/| - File #2 MAIN_PRGRM - 320
 -(L)- - File #2 MAIN_PRGRM - 586
 N7:41/2 - -(L)- - File #2 MAIN_PRGRM - 586
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/15 - -(U)- - File #2 MAIN_PRGRM - 586
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

MOTOR 19
REVERSE
M19R

83

(U)

119

MANUAL
MOTOR 19
REVERSE
ENABLE
M19RE

N7:41

(U)

2

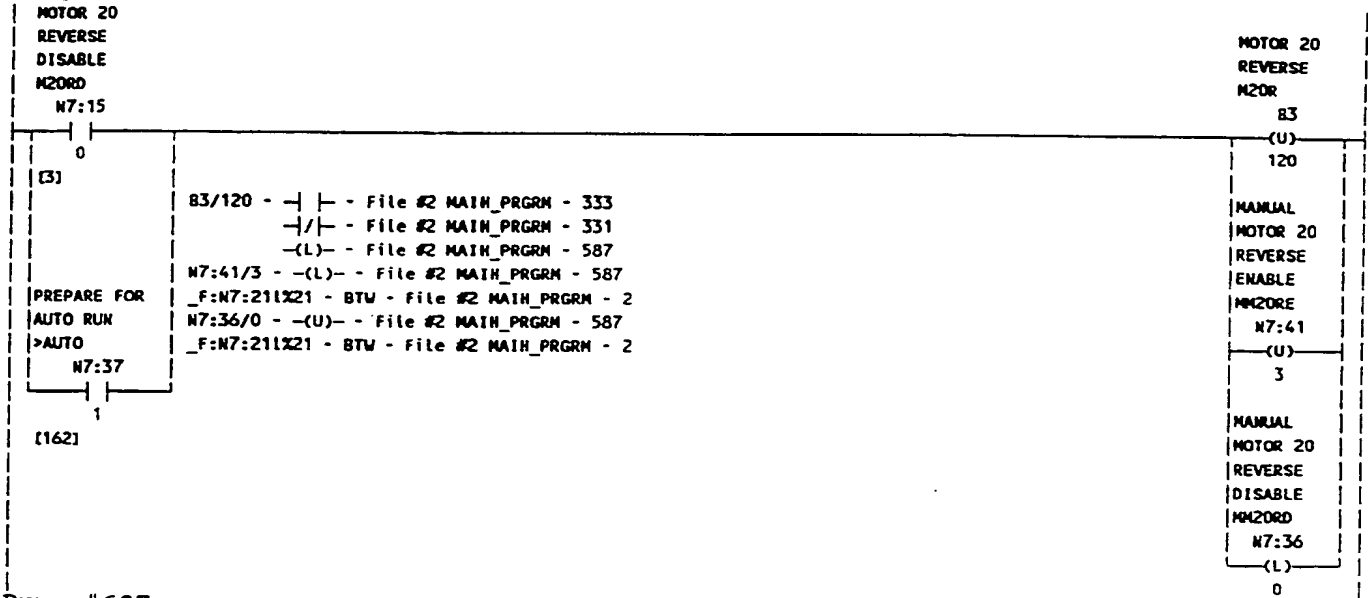
MANUAL
MOTOR 19
REVERSE
DISABLE
M19RD

N7:35

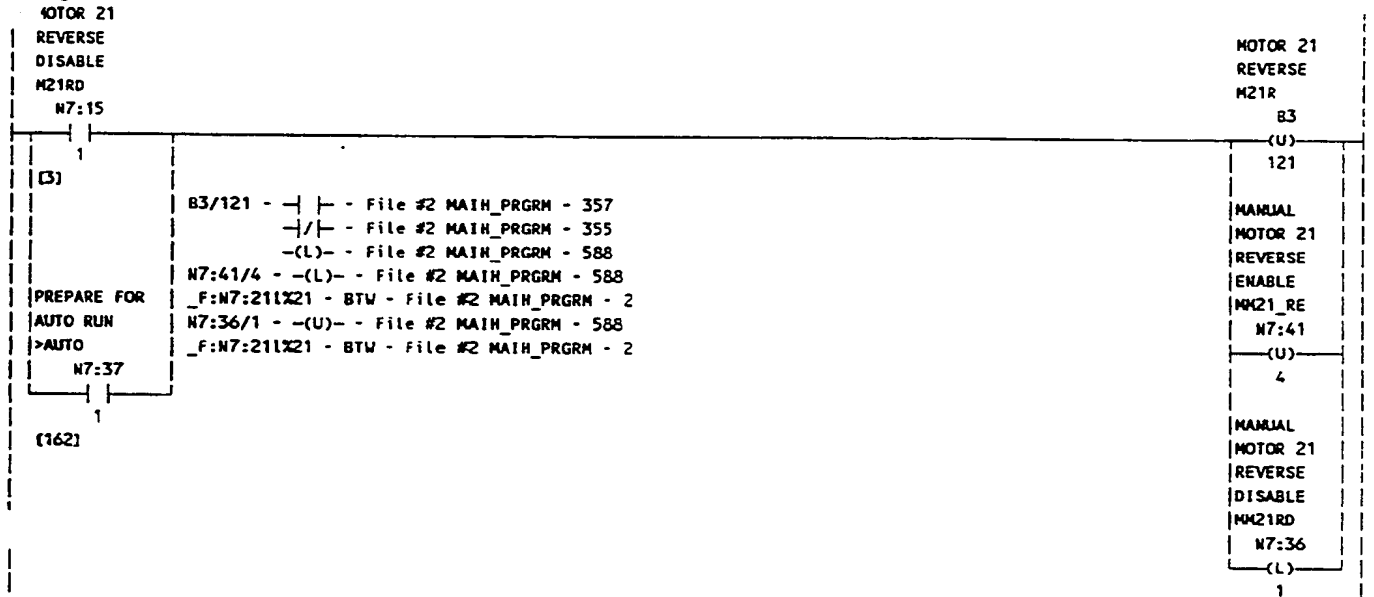
(L)

15

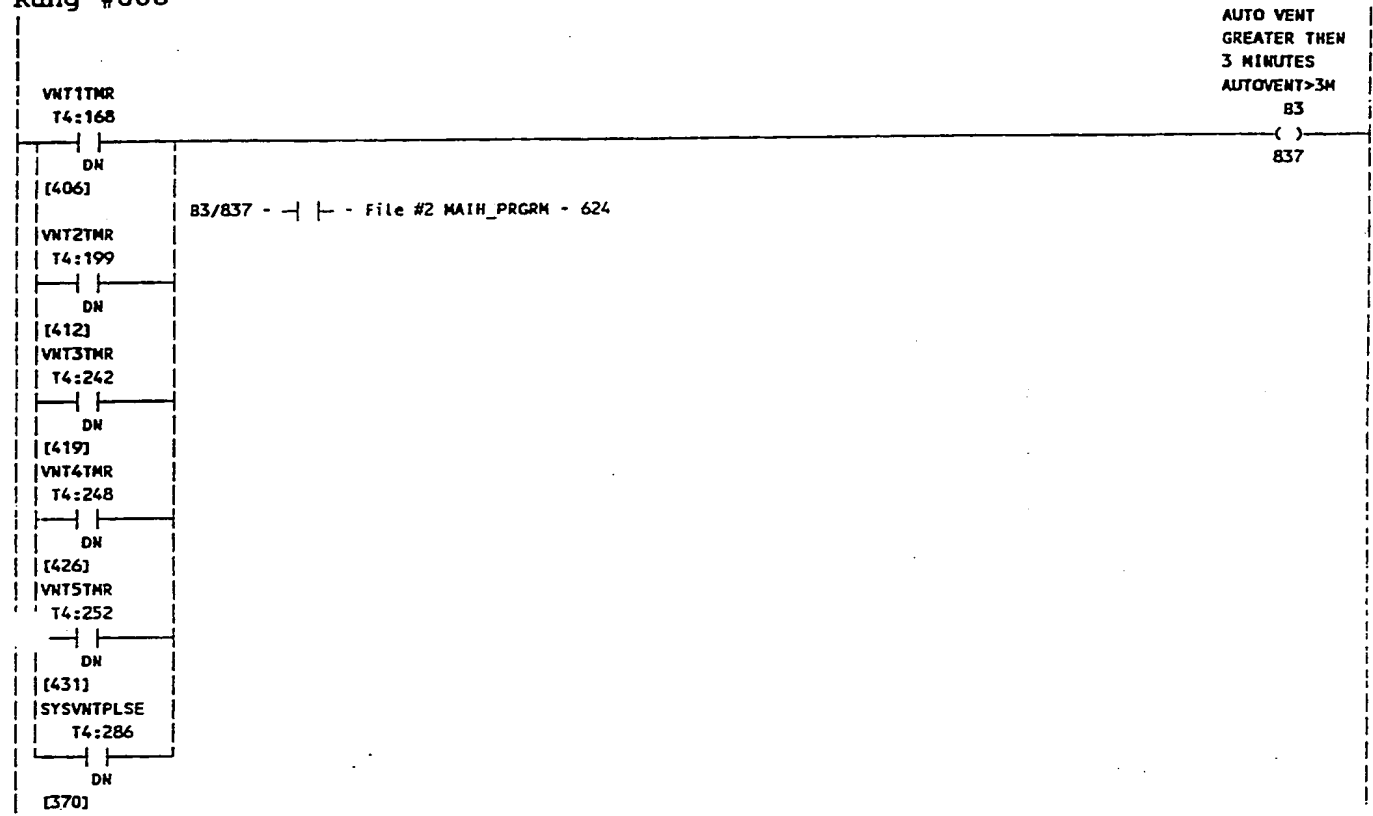
Rung #606



Rung #607

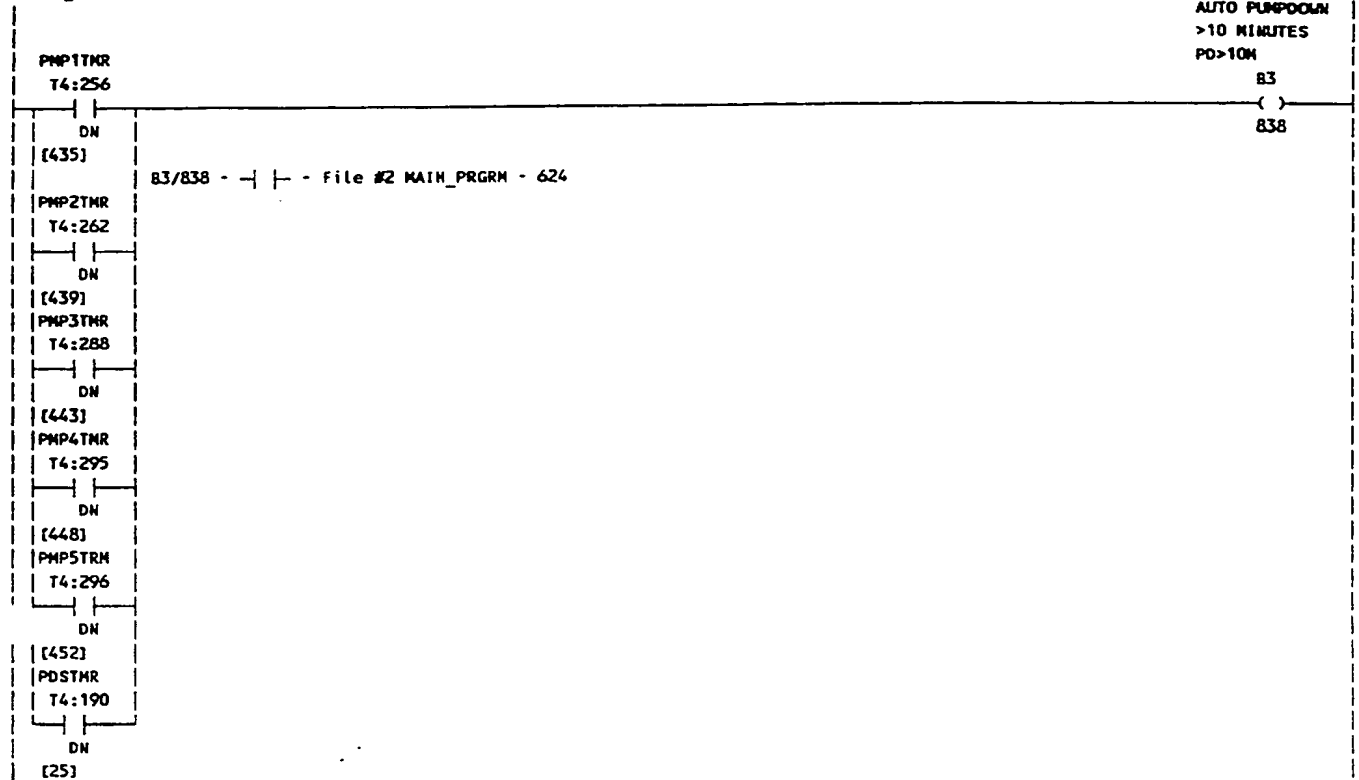


Rung #608



387

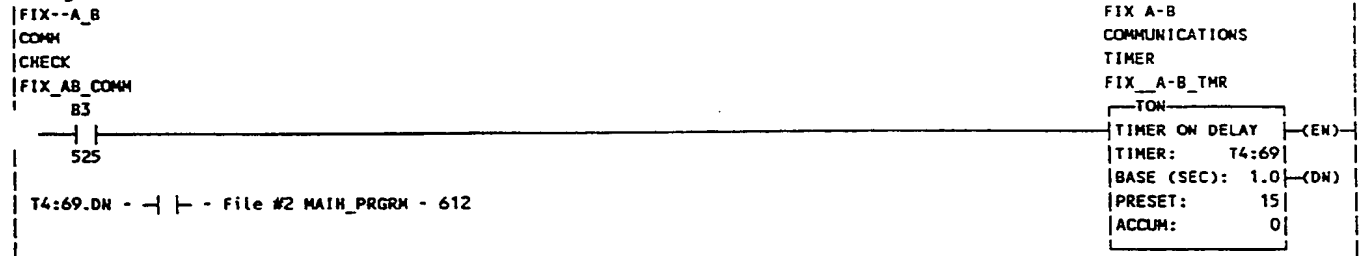
Rung #609



Rung #610



Rung #611

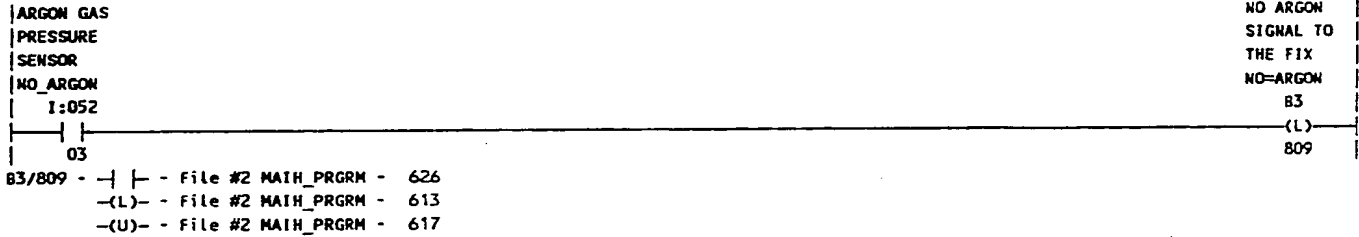


388

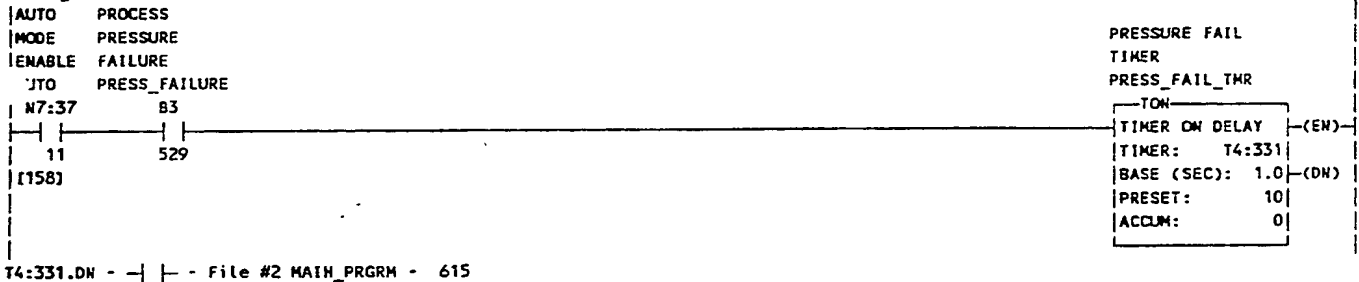
Rung #612



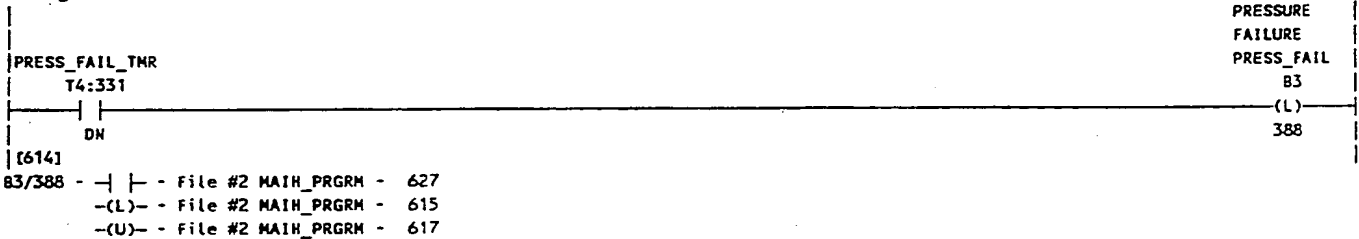
Rung #613



Rung #614



Rung #615



Rung #616



Rung #617

| PAUSE
| DISABLE
| TS12

| N7:16

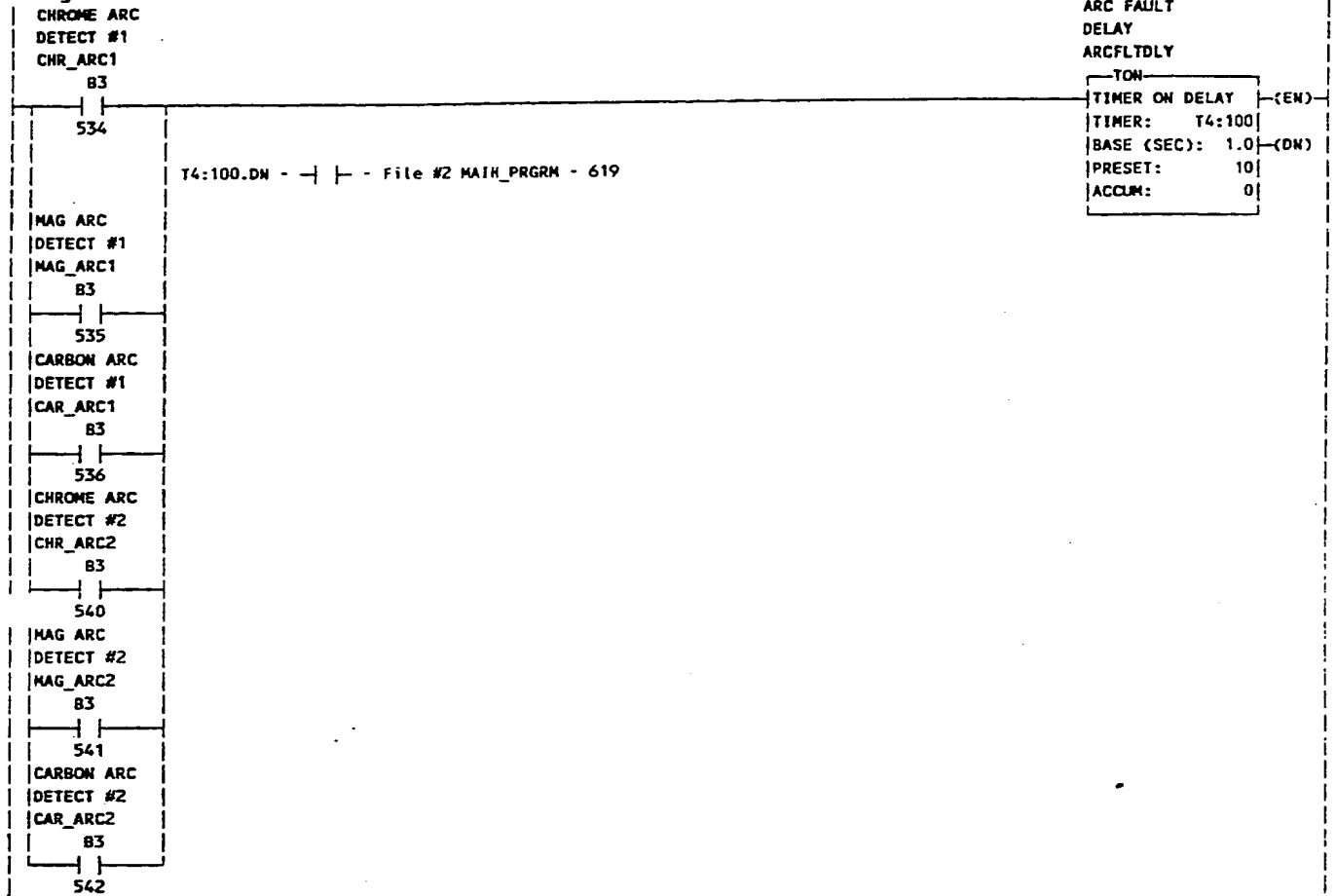
| 4

| [3]

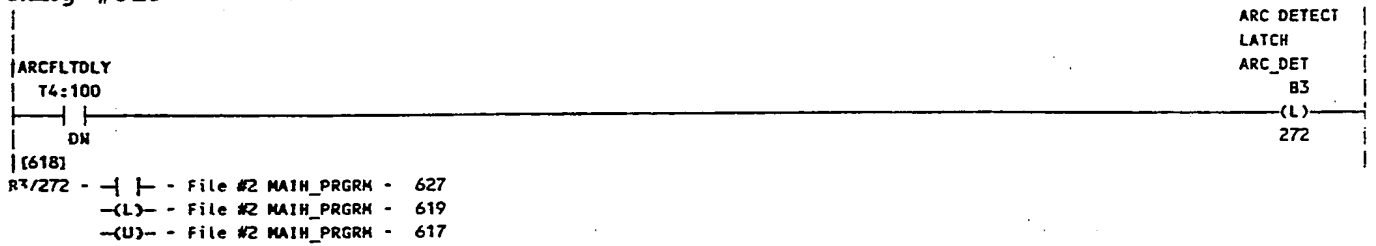
B3/387 - | | - File #2 MAIN_PRGRM - 627
 -(L)- - File #2 MAIN_PRGRM - 616
B3/388 - | | - File #2 MAIN_PRGRM - 627
 -(L)- - File #2 MAIN_PRGRM - 615
B3/272 - | | - File #2 MAIN_PRGRM - 627
 -(L)- - File #2 MAIN_PRGRM - 619
B3/809 - | | - File #2 MAIN_PRGRM - 626
 -(L)- - File #2 MAIN_PRGRM - 613
B3/810 - | | - File #2 MAIN_PRGRM - 626
 -(L)- - File #2 MAIN_PRGRM - 612

NO_ARGON
LATCH
NO_ARGONLATCH
B3(U)
387PRESSURE
FAILURE
PRESS_FAIL
B3(U)
388ARC DETECT
LATCH
ARC_DET
B3(U)
272NO ARGON
SIGNAL TO
THE FIX
NO=ARGONB3
(U)809
FIX_A-B
COMMUNICATIONS
LOST!NO_FX_A-B_COMM
B3(U)
810

Rung #618

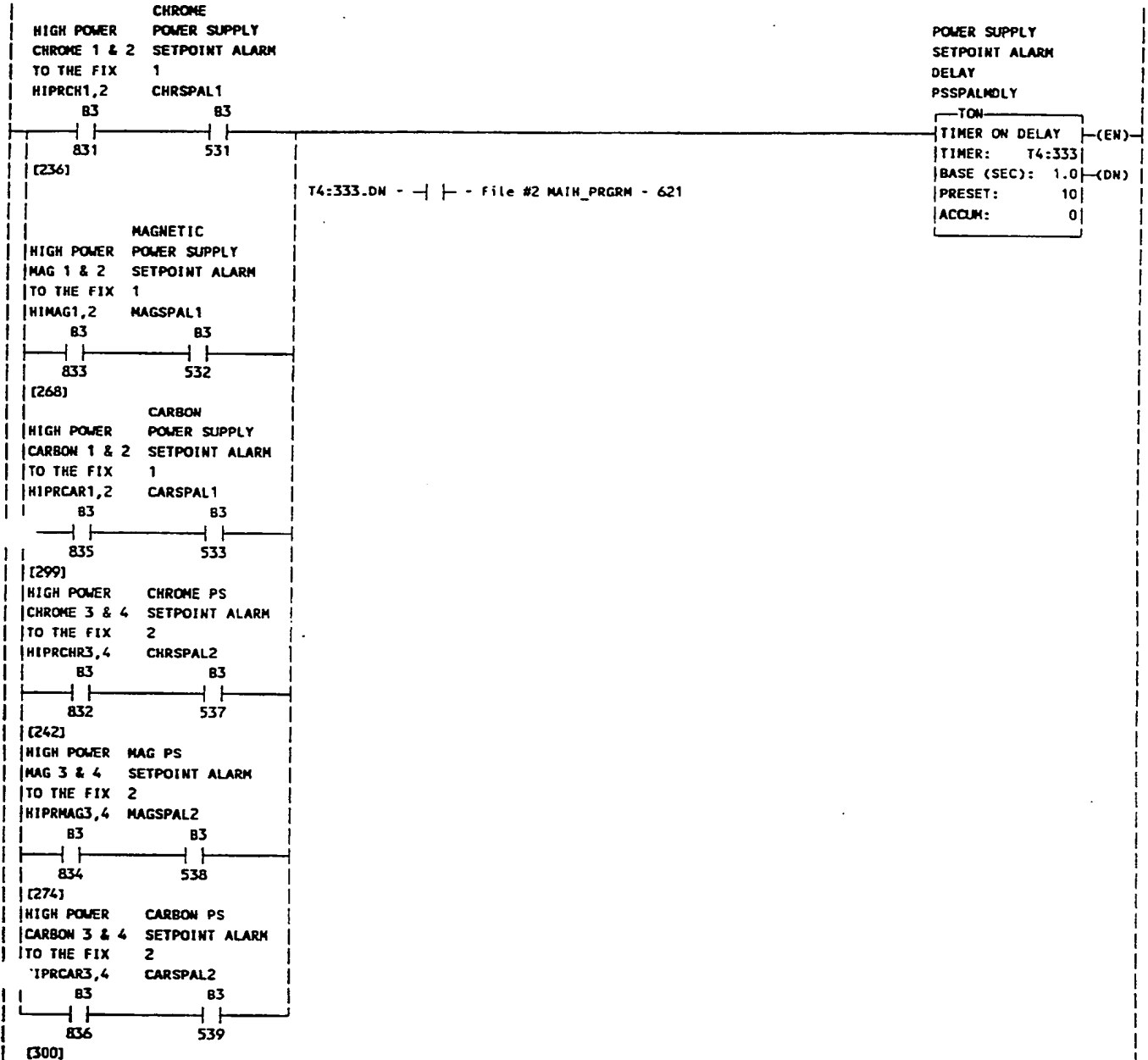


Rung #619

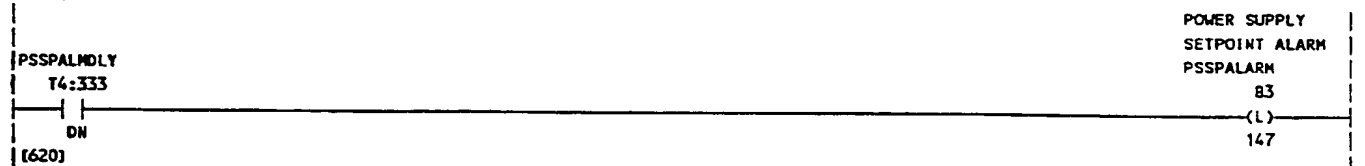


391

Rung #620



Rung #621



392

83/147 - | | - File #2 MAIN_PRGRM - 625
-(L)- - File #2 MAIN_PRGRM - 621
-(U)- - File #2 MAIN_PRGRM - 629

Rung #622

HIGH POWER
CHROME 1 & 2
TO THE FIX
HIPRCH1,2

83

831

[236]
HIGH POWER
CHROME 3 & 4
TO THE FIX
HIPRCHR3,4

83

832

[242]
HIGH POWER
MAG 1 & 2
TO THE FIX
HIMAG1,2

83

833

[268]
HIGH POWER
MAG 3 & 4
TO THE FIX
HIPRMAG3,4

83

834

[274]
HIGH POWER
CARBON 1 & 2
TO THE FIX
HIPRCAR1,2

83

835

[299]
HIGH POWER
CARBON 3 & 4
TO THE FIX
HIPRCAR3,4

83

836

[300]

POWER SUPPLY
HIGH POWER
ON
HIPWON

83

301

393

Rung #623

RERUF GREATER
THAN 10
TIMES
RERUF>10
83
()
819

C1RERUF
CS:1

DN

[3:19]

83/819 - - - File #2 MATH_PRGRM - 624

C2RERUF
CS:2

DN

[3:196]

C2RERUF
CS:2

DN

[3:196]

C3RERUF
CS:3

DN

[3:197]

C4RERUF
CS:4

DN

[3:198]

C5RERUF
CS:5

DN

[3:199]

C6R3RUF
CS:6

DN

[3:200]

C7RERUF
CS:7

DN

[3:201]

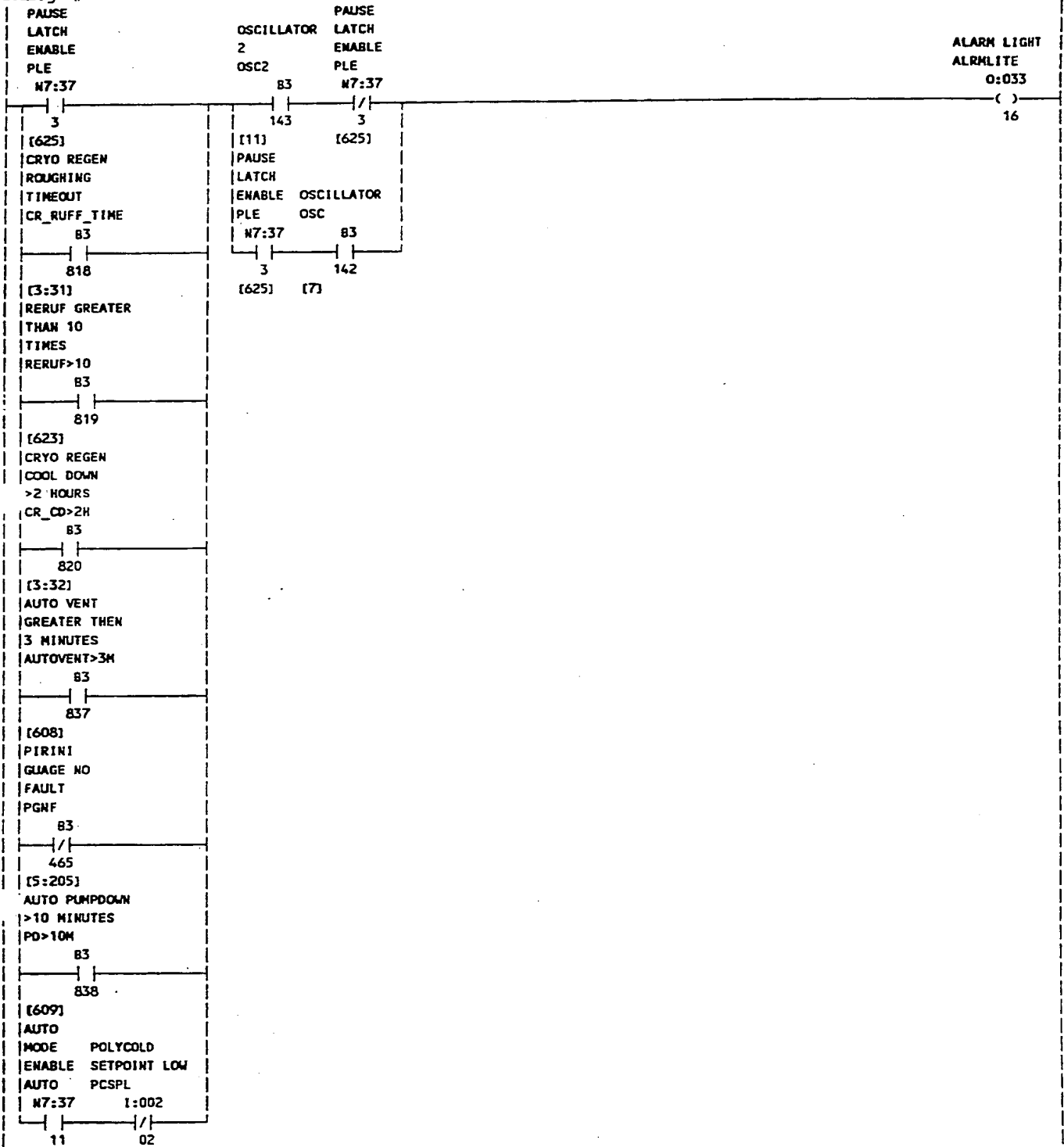
C8RERUF
CS:8

DN

[3:202]

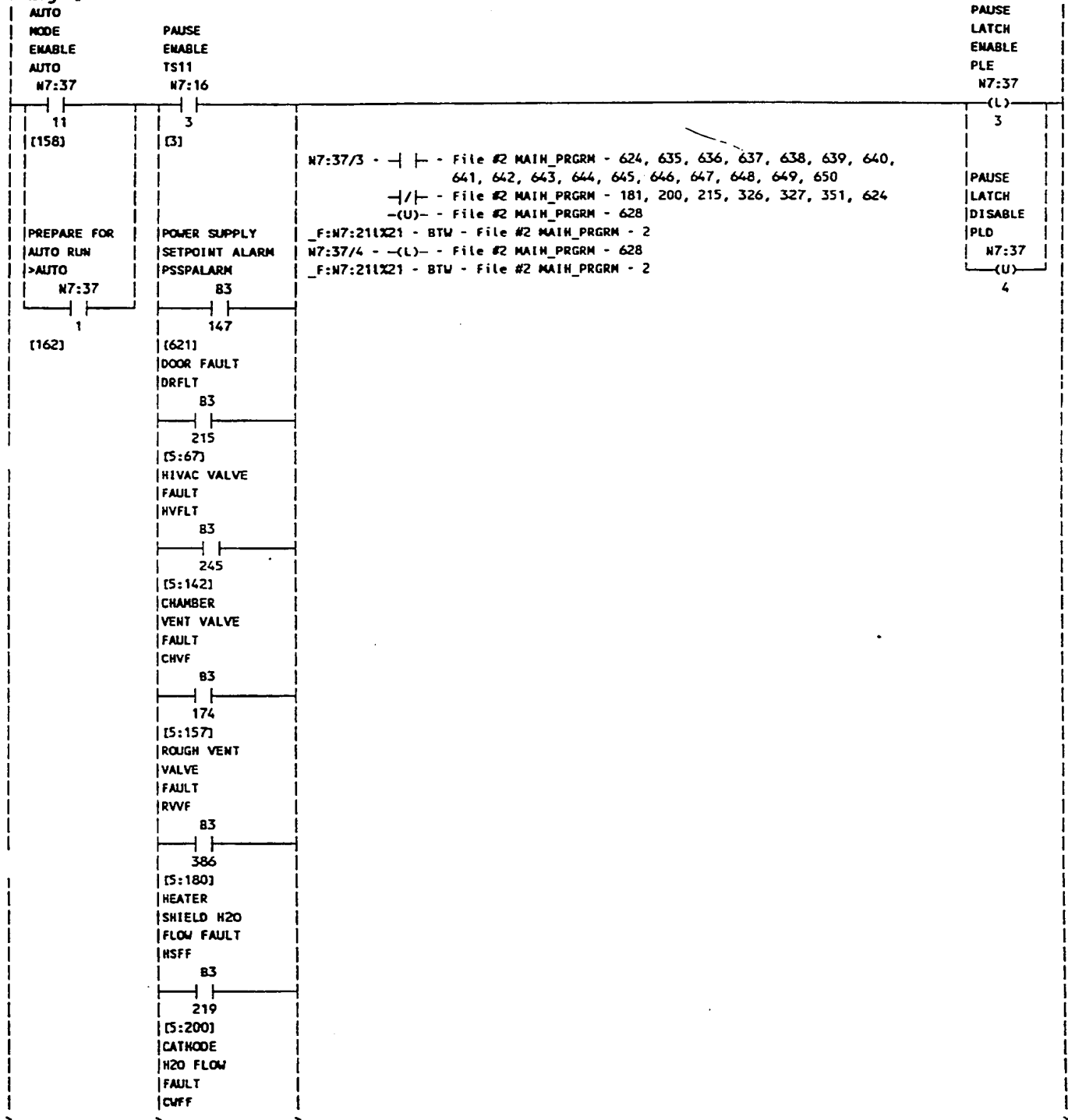
394

Rung #624

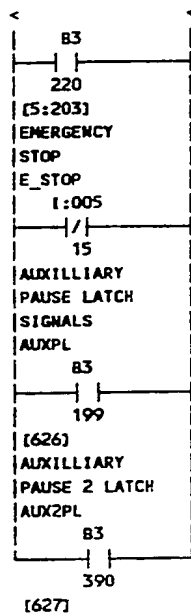


395

[158]
Rung #625



396



Rung #626

NO ARGON
SIGNAL TO
THE FIX
NO=ARGON
B3

AUXILIARY
PAUSE LATCH
SIGNALS
AUXPL

B3

809

[617]

FIX_A-B
COMMUNICATIONS
LOST1
NO_FIX_A-B_COMM

B3

[AF1]

810

[617]

MOTOR FAULT
TIMER DONE

MOTOR_FLT

B3

811

[5:15]

CHAMBER

NOT AT

/VACUUM

NO_VACUUM

B3

812

[633]

CRYO TEMP

ABOVE 20K

CRYO_>20K

B3

813

[630]

LOAD LOCK

VENT>30 SECS

LLVNT>30SECS

B3

814

[176]

EXIT LOCK

VENT>30 SECS

EXLVNT>30SECS

B3

815

[349]

LOAD LOCK

ROUGHING

>60 SECONDS

LLRUF>60

B3

816

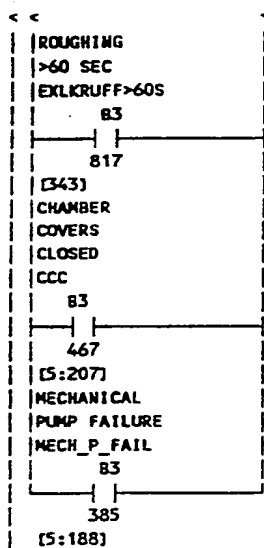
[170]

EXIT LOCK

B3/199 - | - File #2 MAIN_PRGRM - 625

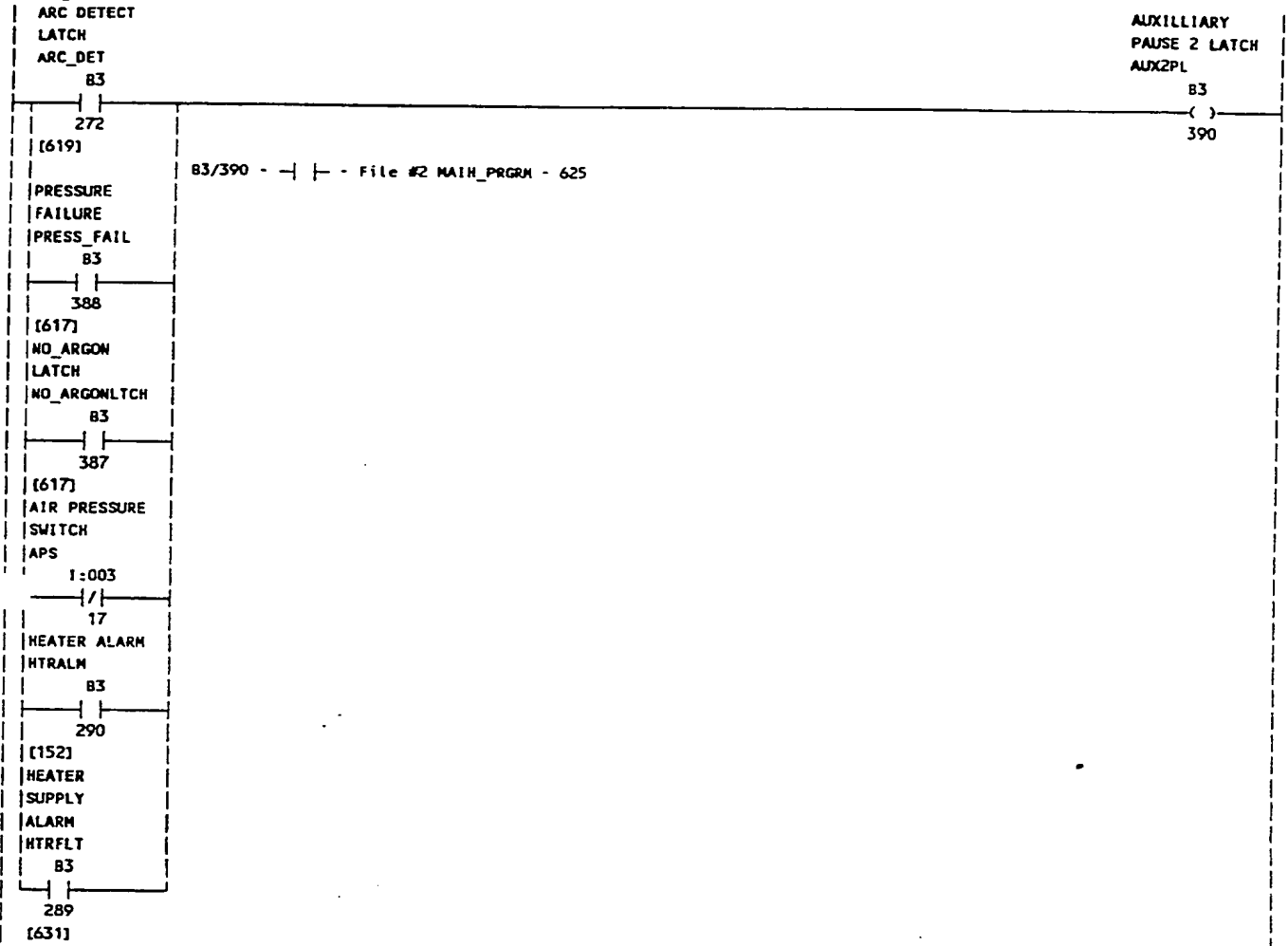
199

39-8



399

Rung #627



400

BASE : Rung #628

ARC DETECT
LATCH
ARC_DET

AUXILLIARY
PAUSE 2 LATCH
AUX2PL

83

83

272

()
390

[620]

83/390 - - File #2 MAIN_PRGRM - 626

PRESSURE
FAILURE
PRESS_FAIL

83

388

[618]

NO_ARGON
LATCH
NO_ARGONLATCH

83

387

[618]

AIR PRESSURE
SWITCH
APS

I:003

17

HEATER ALARM
HTRALM

83

[AFI]

290

[152]

HEATER
SUPPLY
ALARM
HTRFLT

83

289

[632]

401

Rung #629

PAUSE
 DISABLE
 TS12

N7:16

4

(3)

83/147 - | | - File #2 MAIN_PRGRM - 625
 -(L)- - File #2 MAIN_PRGRM - 621
 83/474 - | | - File #2 MAIN_PRGRM - 218
 -(L)- - File #2 MAIN_PRGRM - 638
 83/475 - | | - File #2 MAIN_PRGRM - 258
 -(L)- - File #2 MAIN_PRGRM - 641
 83/476 - | | - File #2 MAIN_PRGRM - 290
 -(L)- - File #2 MAIN_PRGRM - 644
 83/477 - | | - File #2 MAIN_PRGRM - 315
 -(L)- - File #2 MAIN_PRGRM - 647

POWER SUPPLY
 SETPOINT ALARM
 PSSPALARM

83

(U)

147

STOP MOTOR 6
 PAUSE LATCH
 M6PL

83

(U)

474

STOP MOTOR 10
 PAUSE LATCH
 M10PL

83

(U)

475

STOP MOTOR 14
 PAUSE LATCH
 M14PL

83

(U)

476

STOP MOTOR 18
 PAUSE LATCH
 M18PL

83

(U)

477

402

Rung #630

AUTO CRYO 1
 MODE TEMPERATUR
 ENABLE =<20K
 AUTO CY1TMP20
 N7:37 83

CRYO TEMP
 ABOVE 20K
 CRYO >20K

11 83
 501 (L)
 813
 (158)

83/813 - | | - File #2 MAIN_PRGRM - 626
 -(U)- - File #2 MAIN_PRGRM - 632

CRYO 2
 TEMPERATUR
 =<20K
 CY2TMP20
 83

502

CRYO 3
 TEMPERATUR
 =<20K
 CY3TMP20
 83

503

CRYO 4
 TEMPERATUR
 =<20K
 CY4TMP20
 83

504

CRYO 5
 TEMPERATUR
 =<20K
 CY5TMP20
 83

505

CRYO 6
 TEMPERATUR
 =<20K
 CY6TMP20
 83

506

CRYO 7
 TEMPERATUR
 =<20K
 CY7TMP20
 83

507

CRYO 8
 TEMPERATUR
 =<20K
 CY8TMP20
 83

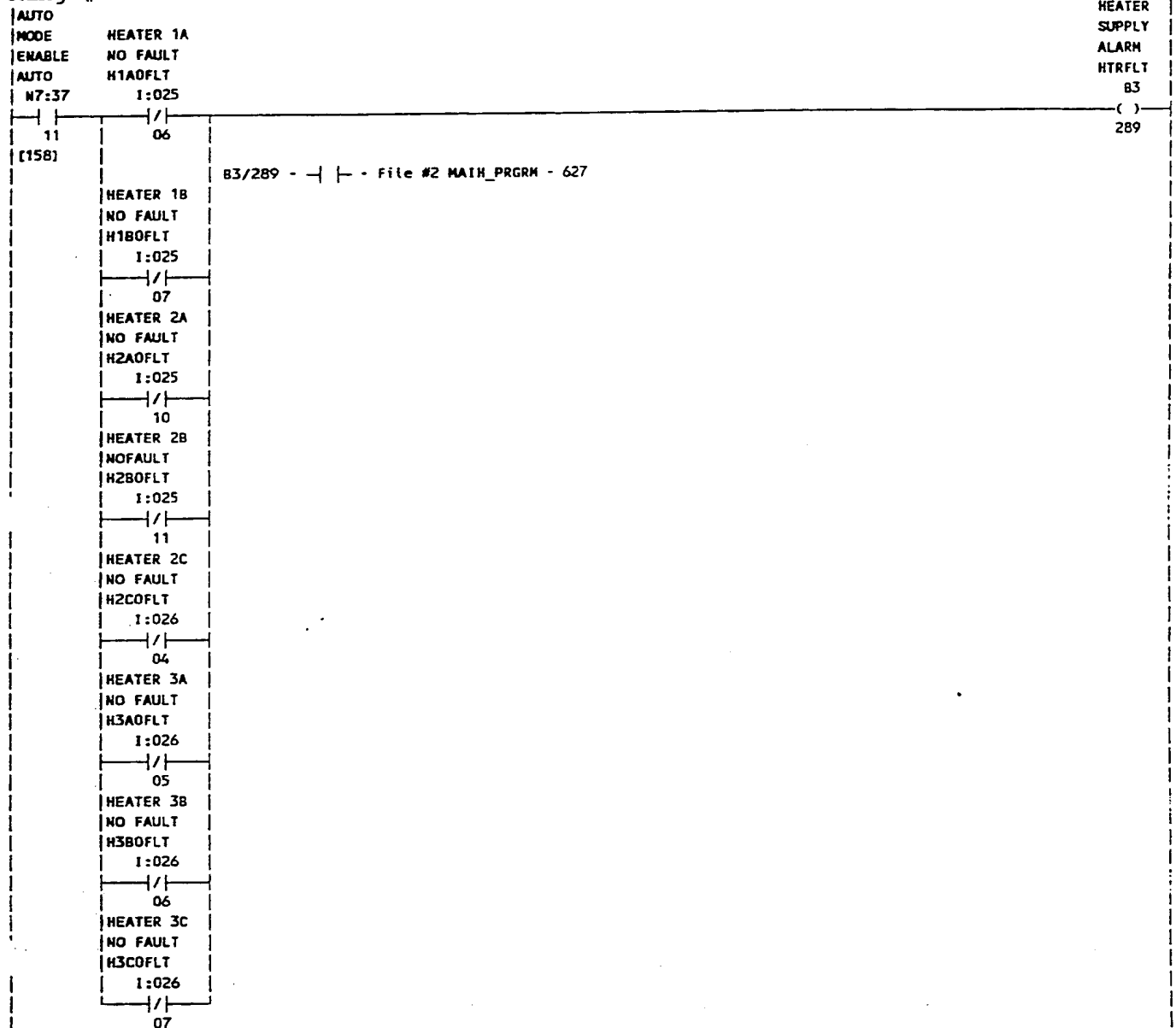
508

CRYO 9
 TEMPERATUR
 =<20K
 CY9TMP20

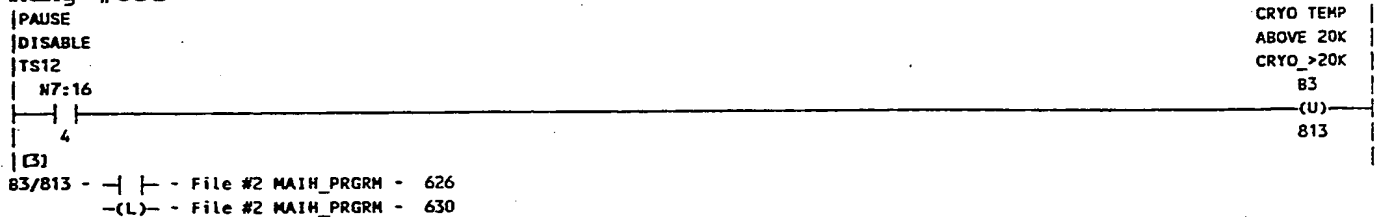
83
509
CRYO 10
TEMPERATUR
=<20K
CY10TMP20
83
510
CRYO 11
TEMPERATUR
=<20K
CY11TMP20
83
511
CRYO 12
TEMPERATUR
=<20K
CY12TMP20
83
512

404

Rung #631

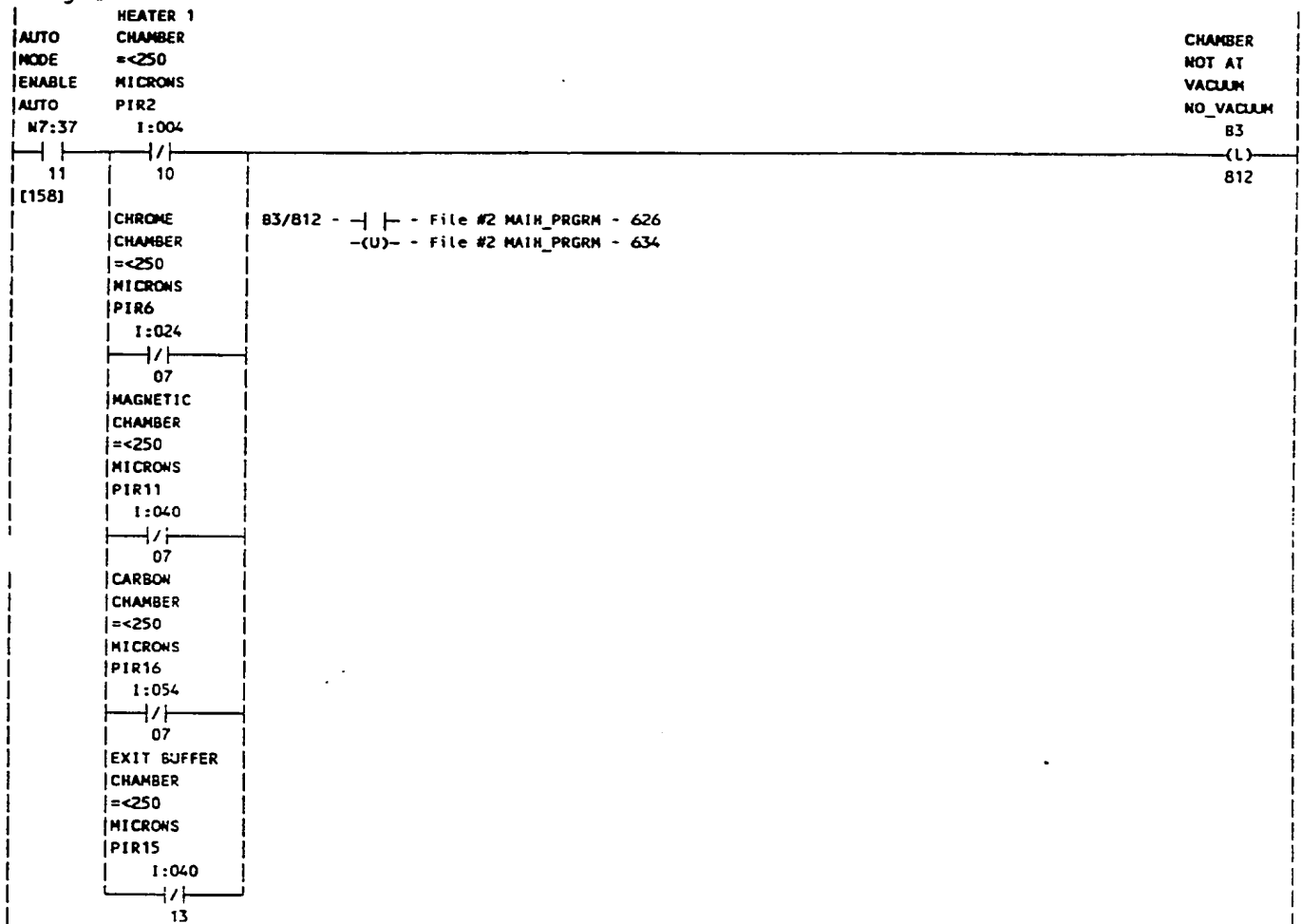


Rung #632



405

-(U)- - File #2 MAIN_PRGRM - 632
Rung #633

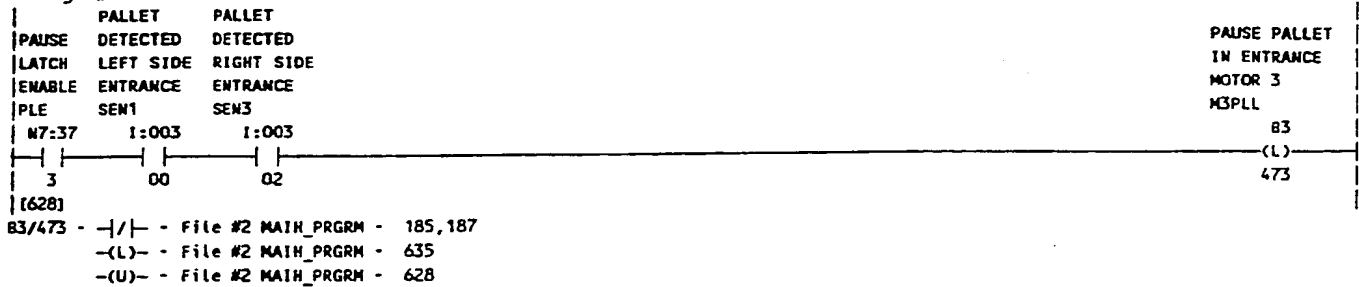


Rung #634

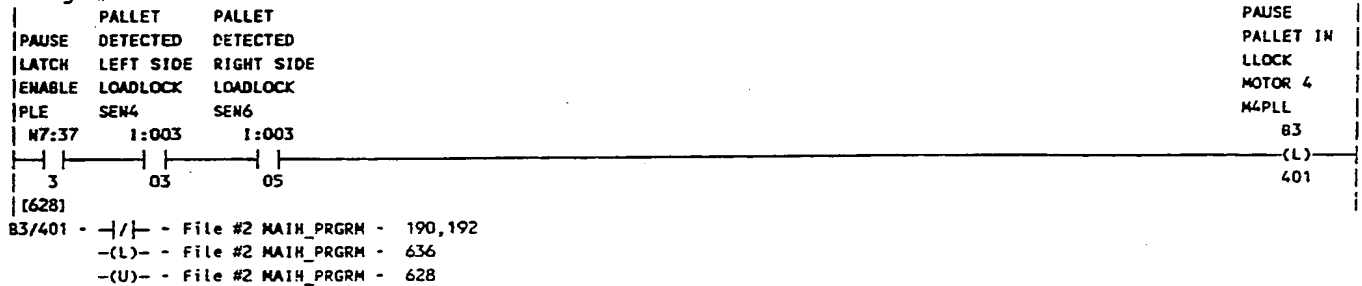


406

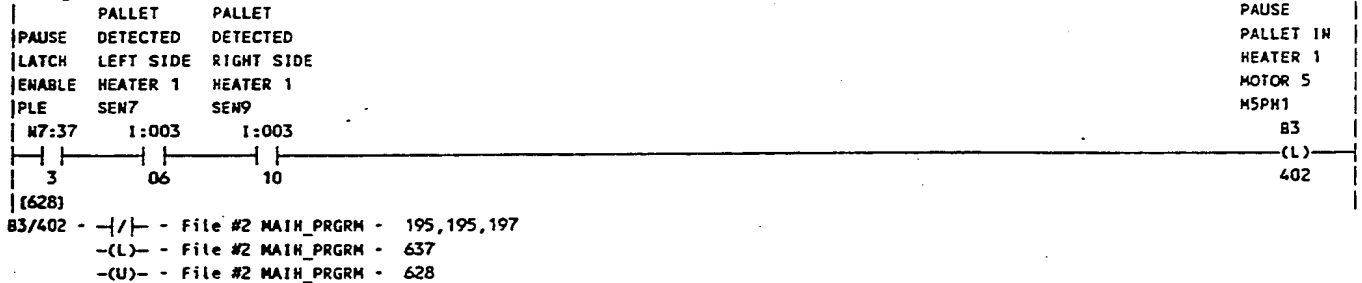
Rung #635



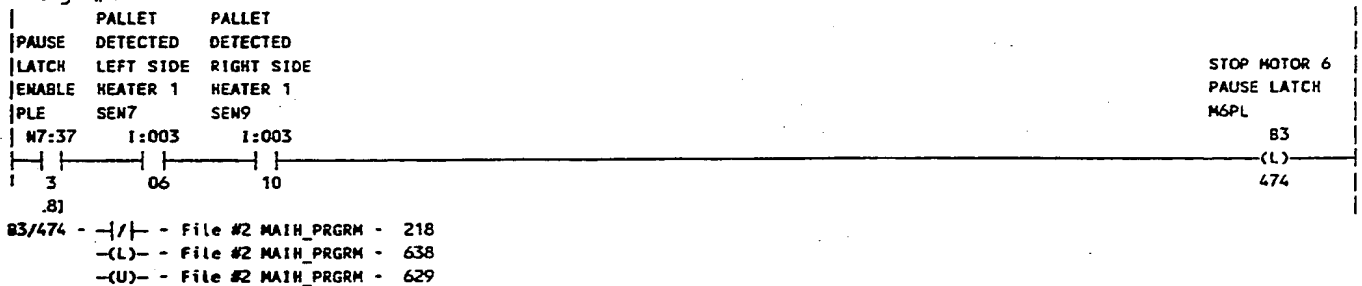
Rung #636



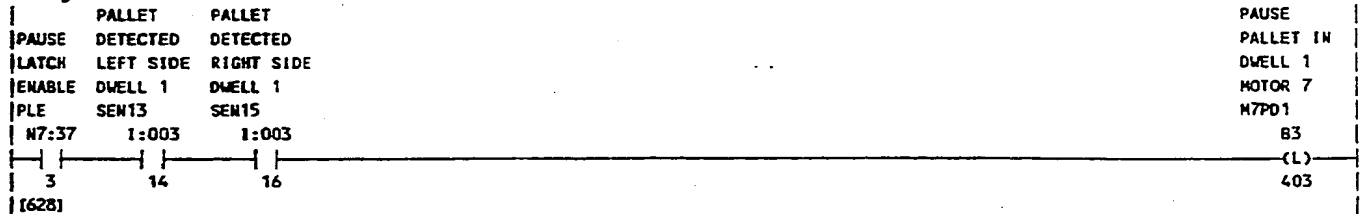
Rung #637



Rung #638



Rung #639



83/403 - \neg /| - File #2 MAIN_PRGRM - 231,231,233
 -(L)- - File #2 MAIN_PRGRM - 639
 -(U)- - File #2 MAIN_PRGRM - 628

Rung #640

	PALLET	PALLET			PAUSE
PAUSE	DETECTED	DETECTED			PALLET IN
LATCH	LEFT SIDE	RIGHT SIDE			DWELL 2
ENABLE	DWELL 2	DWELL 2			MOTOR 9
PLE	SEN19	SEN21			M9PD2
N7:37	1:023	1:023			83
3	03	05			(L)
[628]					404

83/404 - \neg /| - File #2 MAIN_PRGRM - 253,255
 -(L)- - File #2 MAIN_PRGRM - 640
 -(U)- - File #2 MAIN_PRGRM - 628

Rung #641

	PALLET	PALLET			
PAUSE	DETECTED	DETECTED			STOP MOTOR 10
LATCH	LEFT SIDE	RIGHT SIDE			PAUSE LATCH
ENABLE	DWELL 2	DWELL 2			M10PL
PLE	SEN19	SEN21			83
N7:37	1:023	1:023			(L)
3	03	05			475
[628]					

475 - \neg /| - File #2 MAIN_PRGRM - 258
 -(L)- - File #2 MAIN_PRGRM - 641
 -(U)- - File #2 MAIN_PRGRM - 629

Rung #642

	PALLET	PALLET			PAUSE
PAUSE	DETECTED	DETECTED			PALLET IN
LATCH	LEFT SIDE	RIGHT SIDE			DWELL 3
ENABLE	DWELL 3	DWELL 3			MOTOR 11
PLE	SEN25	SEN27			M11PD3
N7:37	1:023	1:023			83
3	11	13			(L)
[628]					405

83/405 - \neg /| - File #2 MAIN_PRGRM - 263,265
 -(L)- - File #2 MAIN_PRGRM - 642
 -(U)- - File #2 MAIN_PRGRM - 628

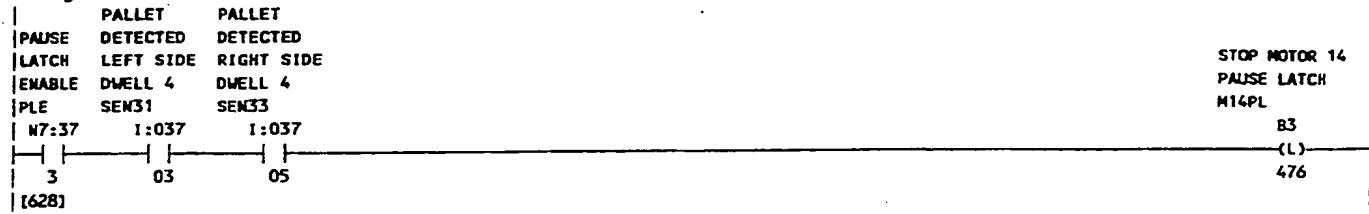
Rung #643

	PALLET	PALLET	PALLET		PAUSE
PAUSE	DETECTED	DETECTED	DETECTED		PALLET IN
LATCH	LEFT SIDE	RIGHT SIDE	CENTER		DWELL 4
ENABLE	DWELL 4	DWELL 4	MAGNETIC		MOTOR 13
PLE	SEN31	SEN33	SEN29		M13PD4
N7:37	1:037	1:037	1:037		83
3	03	05	01		(L)
[628]					406

83/406 - \neg /| - File #2 MAIN_PRGRM - 285,287
 -(L)- - File #2 MAIN_PRGRM - 643
 -(U)- - File #2 MAIN_PRGRM - 628

408

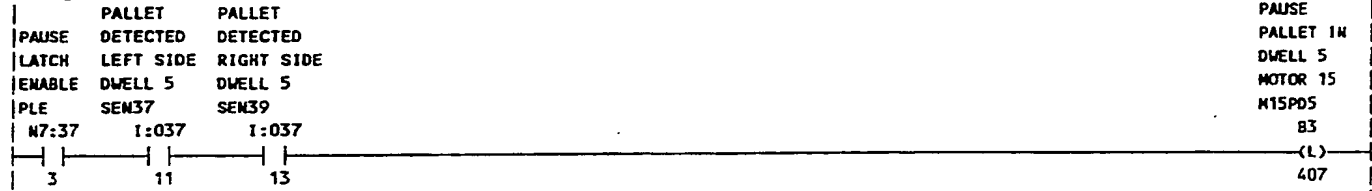
Rung #644



[628]

B3/476 - | / | - File #2 MAIN_PRGRM - 290
 -(L)- File #2 MAIN_PRGRM - 644
 -(U)- File #2 MAIN_PRGRM - 629

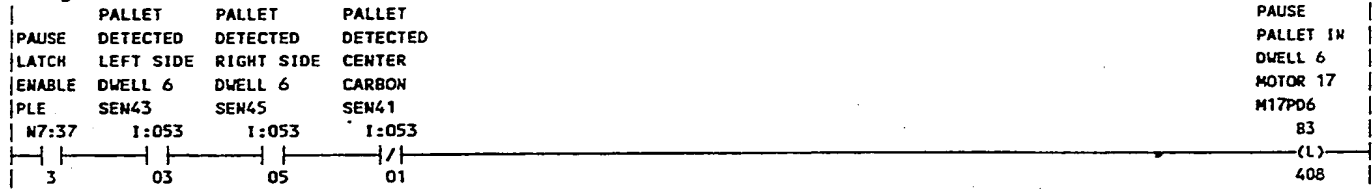
Rung #645



[628]

B3/407 - | / | - File #2 MAIN_PRGRM - 295,297
 -(L)- File #2 MAIN_PRGRM - 645
 -(U)- File #2 MAIN_PRGRM - 628

Rung #646



[628]

B3/408 - | / | - File #2 MAIN_PRGRM - 310,312
 -(L)- File #2 MAIN_PRGRM - 646
 -(U)- File #2 MAIN_PRGRM - 628

Rung #647



[628]

B3/477 - | / | - File #2 MAIN_PRGRM - 315
 -(L)- File #2 MAIN_PRGRM - 647
 -(U)- File #2 MAIN_PRGRM - 629

Rung #648



[628]

B3/409 - -|/| - File #2 MAIN_PRGRM - 320,322
 -(L)- - File #2 MAIN_PRGRM - 648
 -(U)- - File #2 MAIN_PRGRM - 628

Rung #649

	PALLET	PALLET		PAUSE PALLET
PAUSE	DETECTED	DETECTED		EXITLOCK
LATCH	LEFT SIDE	RIGHT SIDE		MOTOR 20
ENABLE	EXIT LOCK	EXLOCK		PAUSE
PLE	SEN52	SEN54		M20PXL
	N7:37	1:053	1:053	83
	3	14	16	(L)
				490

B3/490 - -|/| - File #2 MAIN_PRGRM - 331,333
 -(L)- - File #2 MAIN_PRGRM - 649
 -(U)- - File #2 MAIN_PRGRM - 628

Rung #650

	PALLET	PALLET		PAUSE
PAUSE	DETECTED	DETECTED		PALLET AT
LATCH	LEFT SIDE	RIGHT SIDE		EXIT
ENABLE	EXIT END	EXIT END		MOTOR 21
PLE	SEN55	SEN57		M21PPX
	N7:37	1:053	1:054	83
	3	17	17	(L)
				410

'410 - -|/| - File #2 MAIN_PRGRM - 355,357
 -(L)- - File #2 MAIN_PRGRM - 650
 -(U)- - File #2 MAIN_PRGRM - 628

Rung #651

	LLOCK			SCREEN
CHAMBER				AREA 1
PRESSUR AT				VENTED
ATMOSPHERE				V1DN
PS2				83
	1:002			(L)
	04			821

B3/821 - -(L)- - File #2 MAIN_PRGRM - 651
 -(U)- - File #2 MAIN_PRGRM - 652

Rung #652

	HEATER 1			SCREEN
CHAMBER				AREA 1
<250				VENTED
MICROWS				V1DN
PIR2				83
	1:004			(U)
	10			821

B3/821 - -(L)- - File #2 MAIN_PRGRM - 651
 -(U)- - File #2 MAIN_PRGRM - 652

Rung #653

	DWELL 1			SCREEN
CHAMBER				AREA 1
PRESSUR AT				VENTED
ATMOSPHERE				V2DN
PS3				83
	1:002			(L)
	05			822

B3/822 - -(L)- - File #2 MAIN_PRGRM - 653
 -(U)- - File #2 MAIN_PRGRM - 654

410

Rung #654

CHROME
CHAMBER
I=<250
MICRONS
PIR6
1:024

SCREEN
AREA 1
VENTED
V2DN
83

07

(U)
822

83/822 - (L) - File #2 MATH_PRGRM - 653
-(U) - File #2 MATH_PRGRM - 654

Rung #655

DWELL 3
CHAMBER
PRESSUR AT
ATMOSPHERE
PS4
1:022

SCREEN
AREA 3
VENTED
V3DN
83

04

(L)
823

83/823 - (L) - File #2 MATH_PRGRM - 655
-(U) - File #2 MATH_PRGRM - 656

Rung #656

MAGNETIC
CHAMBER
I=<250
CROWS
PIR11
1:040

SCREEN
AREA 3
VENTED
V3DN
83

07

(U)
823

83/823 - (L) - File #2 MATH_PRGRM - 655
-(U) - File #2 MATH_PRGRM - 656

Rung #657

DWELL 5
CHAMBER
PRESSUR AT
ATMOSPHERE
PS5
1:036

SCREEN
AREA 4
VENTED
V4DN
83

04

(L)
824

83/824 - (L) - File #2 MATH_PRGRM - 657
-(U) - File #2 MATH_PRGRM - 658

Rung #658

CARBON
CHAMBER
I=<250
CROWS
PIR16
1:054

SCREEN
AREA 4
VENTED
V4DN
83

07

(U)
824

83/824 - (L) - File #2 MATH_PRGRM - 657
-(U) - File #2 MATH_PRGRM - 658

Rung #659

EXLOCK
CHAMBER
PRESSUR AT
ATMOSPHERE
PS6
1:052

SCREEN
AREA 5
VENTED
V5DN
83

07

(L)

< 04 825
B3/825 - (L)- - File #2 MAIN_PRGRM - 659
 -(U)- - File #2 MAIN_PRGRM - 660
Rung #660
|EXIT BUFFER
|CHAMBER
|= <250
|MICRONS
|PIR15
| 1:040
| 13
B3/825 - (L)- - File #2 MAIN_PRGRM - 659
 -(U)- - File #2 MAIN_PRGRM - 660
Rung #661
|HEATER 1
|CHAMBER
|= <250
|MICRONS
|PIR2
| 1:004
| 10
B3/826 - (L)- - File #2 MAIN_PRGRM - 661
 -(U)- - File #2 MAIN_PRGRM - 662
Rung #662
|LLOCK
|CHAMBER
|PRESSUR AT
|ATMOSPHERE
|PS2
| 1:002
| 04
B3/826 - (L)- - File #2 MAIN_PRGRM - 661
 -(U)- - File #2 MAIN_PRGRM - 662
Rung #663
|CHROME
|CHAMBER
|= <250
|MICRONS
|PIR6
| 1:024
| 07
B3/827 - (L)- - File #2 MAIN_PRGRM - 663
 -(U)- - File #2 MAIN_PRGRM - 664
Rung #664
|WELL 1
|CHAMBER
|PRESSUR AT
|ATMOSPHERE
|PS3
| 1:002
| 05
B3/827 - (L)- - File #2 MAIN_PRGRM - 663
 -(U)- - File #2 MAIN_PRGRM - 664

SCREEN
AREA 5
VENTED
VSDN
83
(U)
825

SCREEN
AREA 1
PUMPED
P1DN
83
(L)
826

SCREEN
AREA 1
PUMPED
P1DN
83
(U)
826

SCREEN
AREA 2
PUMPED
P2DN
83
(L)
827

SCREEN
AREA 2
PUMPED
P2DN
83
(U)
827

412

Rung #665

MAGNETIC	SCREEN
CHAMBER	AREA 3
=<250	PUMPED
MICRONS	P30N
PIR11	B3
I:040	(L)
07	828

83/828 - (L) - File #2 MAIN_PRGRM - 665
-(U) - File #2 MAIN_PRGRM - 666

Rung #666

DWELL 3	SCREEN
CHAMBER	AREA 3
PRESSUR AT	PUMPED
ATMOSPHERE	P30N
PS4	B3
I:022	(U)
04	828

83/828 - (L) - File #2 MAIN_PRGRM - 665
-(U) - File #2 MAIN_PRGRM - 666

Rung #667

CARBON	SCREEN
CHAMBER	AREA 4
=<250	PUMPED
MICRONS	P40N
PIR16	B3
I:054	(L)
07	829

83/829 - (L) - File #2 MAIN_PRGRM - 667
-(U) - File #2 MAIN_PRGRM - 668

Rung #668

DWELL 5	SCREEN
CHAMBER	AREA 4
PRESSUR AT	PUMPED
ATMOSPHERE	P40N
PS5	B3
I:036	(U)
04	829

83/829 - (L) - File #2 MAIN_PRGRM - 667
-(U) - File #2 MAIN_PRGRM - 668

Rung #669

EXIT BUFFER	SCREEN
CHAMBER	AREA 5
=<250	PUMPED
MICRONS	P50N
PIR15	B3
I:040	(L)
13	830

83/830 - (L) - File #2 MAIN_PRGRM - 669
-(U) - File #2 MAIN_PRGRM - 670

Rung #670

EXLOCK	SCREEN
CHAMBER	AREA 5
PRESSUR AT	PUMPED
ATMOSPHERE	P50N
PS6	B3
I:052	(U)

04
 83/830 - (L) - File #2 MAIN_PRGRM - 669
 (U) - File #2 MAIN_PRGRM - 670

830

Rung #671

MECHANICAL

PUMP 2

TC=<50

MICRONS

PIR10

1:024

13

LINE PRESSURE
 MADE-TC10
 LPM-TC10
 83
 (L)
 250

83/250 - (L) - File #3 CRYO_REGEN - 15,164,165,166,167,168,169,170,171,172,173,174
 File #6 TECH_RUNGS - 15
 (L) - File #2 MAIN_PRGRM - 671
 (U) - File #2 MAIN_PRGRM - 673

Rung #672

MECHANICAL

PUMP 2

TC=<50

MICRONS

PIR10

1:024

13

TC10 FAULT
 DELAY TIMER
 TC10FDT
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:70
 BASE (SEC): 1.0 (DN)
 PRESET: 60
 ACCUM: 60

T4:70.DN - (L) - File #2 MAIN_PRGRM - 673

Rung #673

TC10

TIMEOUT

TC10FDT

T4:70

DN

[672]

LINE PRESSURE
 MADE-TC10
 LPM-TC10
 83
 (U)
 250

83/250 - (L) - File #3 CRYO_REGEN - 15,164,165,166,167,168,169,170,171,172,173,174
 File #6 TECH_RUNGS - 15
 (L) - File #2 MAIN_PRGRM - 671
 (U) - File #2 MAIN_PRGRM - 673

Rung #674

VENT

LOAD LOCK

PUSHBUTTON

VNTLLPB

N7:3

13

[3]

AUTO

MODE

ENABLE

AUTO

N7:37

11

[158]

PALLET

DETECTED

CENTER

LOADLOCK

SENS

I:003

04

[158]

PALLET

DETECTED

RIGHT SIDE

LOADLOCK

SEN6

I:003

05

[158]

PUMP-VENT

CYCLE LOAD

LOCK

PD-VNT-LL

N7:24

14

[676]

LLOCK

CHAMBER

PRESSUR AT

ATMOSPHERE

PS2

I:002

04

[684]

PUMPDOWN

LOADLOCK

PDLL

N7:24

15

[684]

VENT
 LOAD LOCK
 VNT_LL
 N7:24
 (L)
 13

N7:24/13 - (L) - File #2 MAIN_PRGRM - 166,173,202,675
 (L) - File #2 MAIN_PRGRM - 676,684

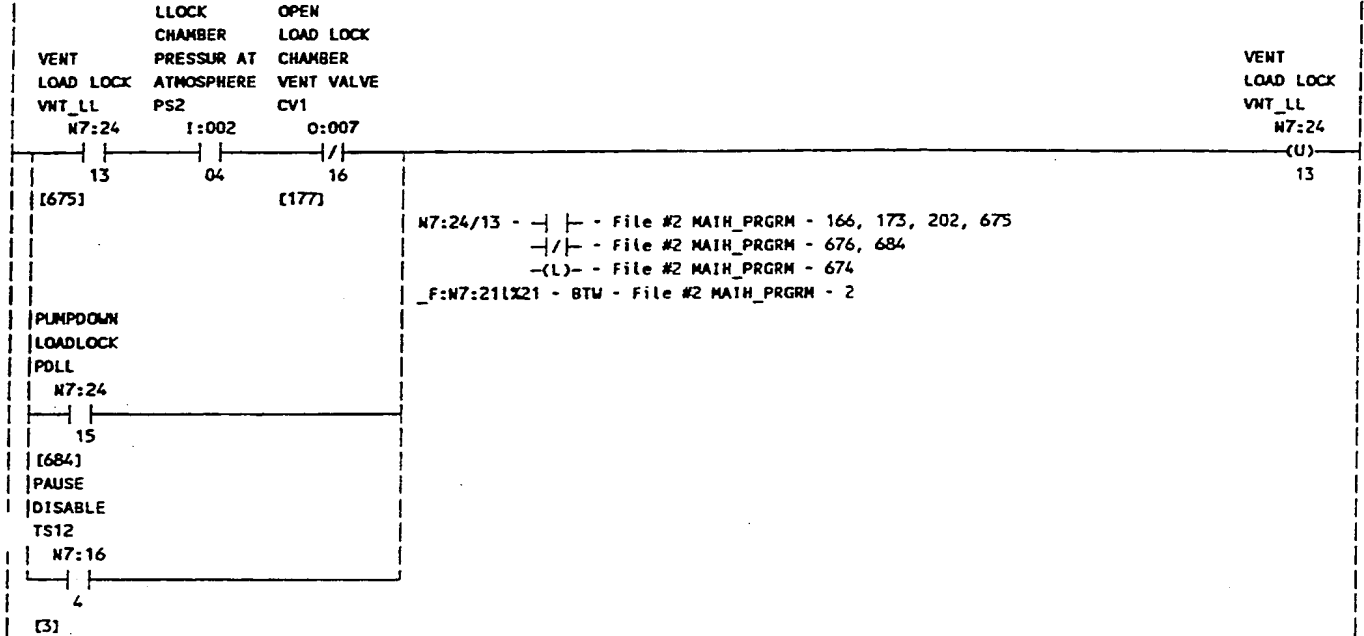
414

-(L)- - File #2 MATH_PRGRM - 674

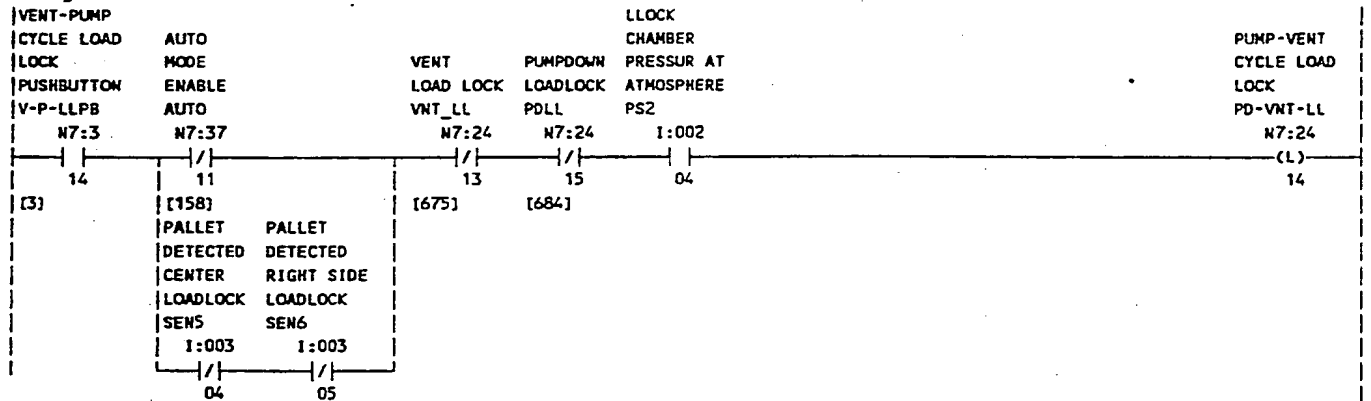
-(U)- - File #2 MATH_PRGRM - 675

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #675



Rung #676



N7:24/14 - | | - File #2 MATH_PRGRM - 68, 166, 181, 677, 678, 679, 680, 681, 682

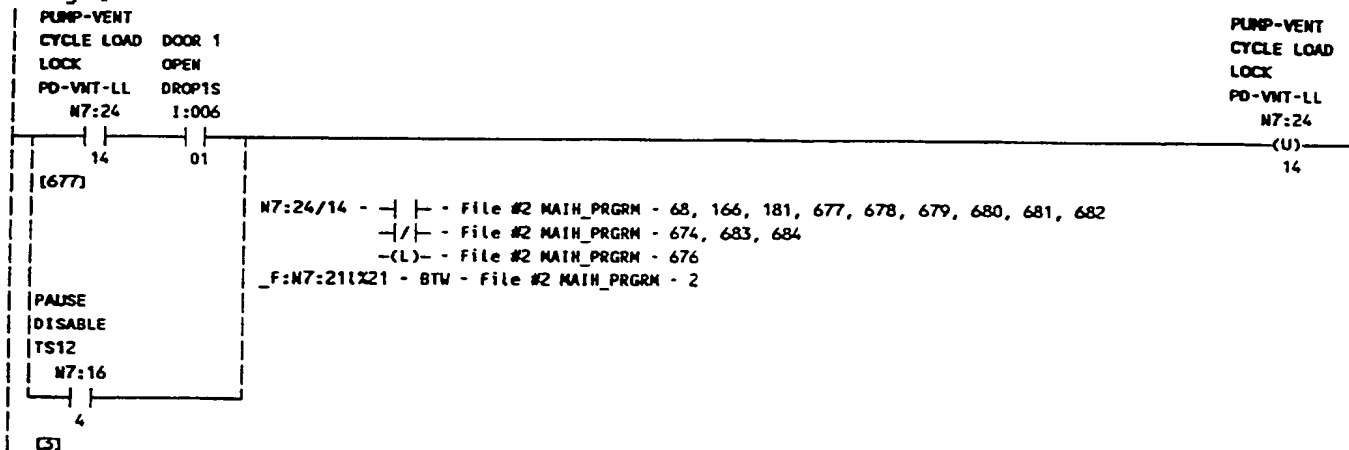
-|/| - File #2 MATH_PRGRM - 674, 683, 684

-(L)- - File #2 MATH_PRGRM - 676

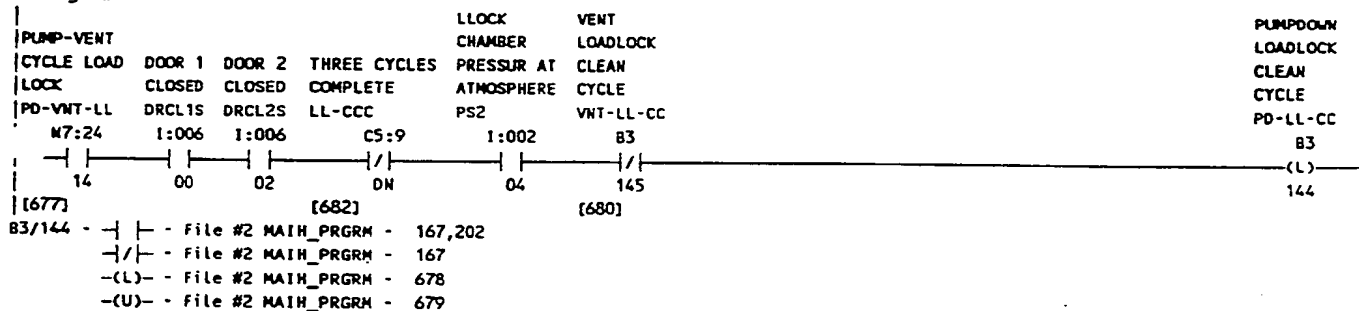
-(U)- - File #2 MATH_PRGRM - 677

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

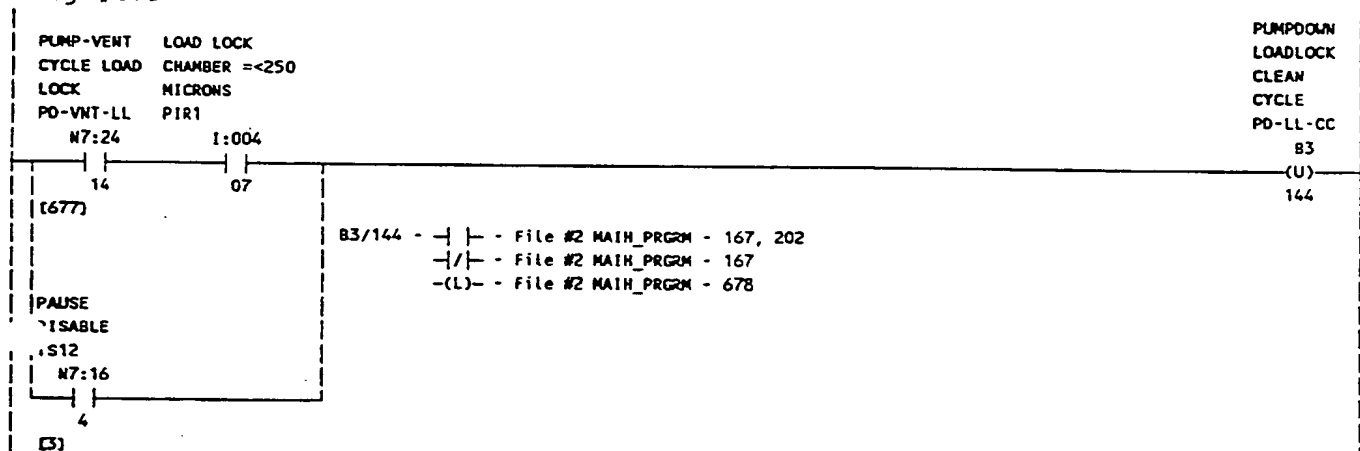
Rung #677



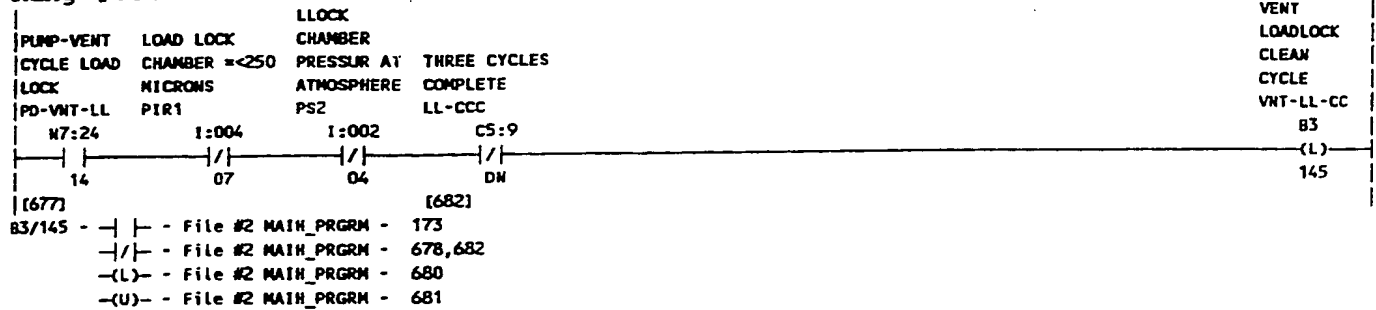
Rung #678



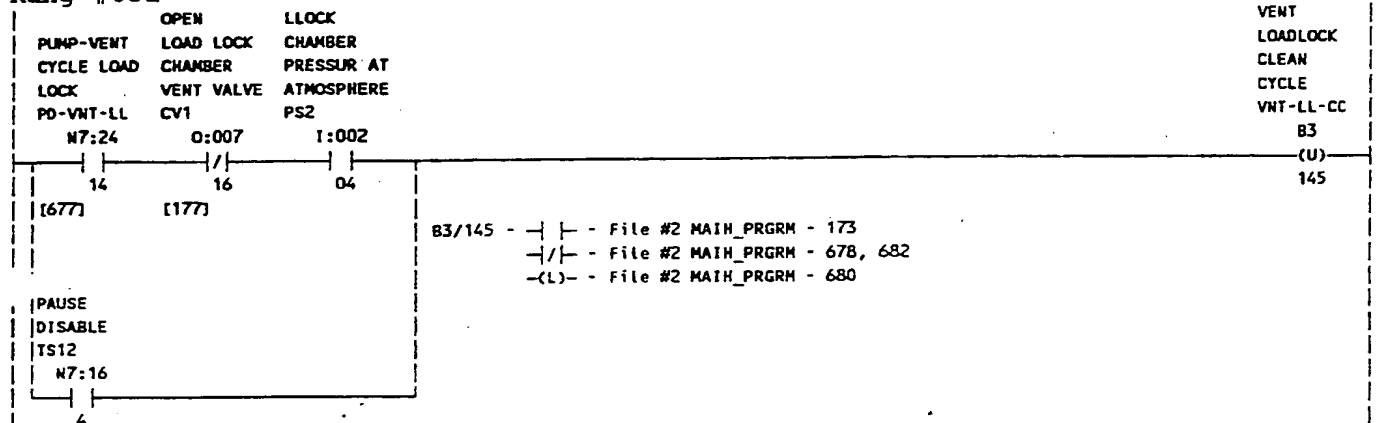
Rung #679



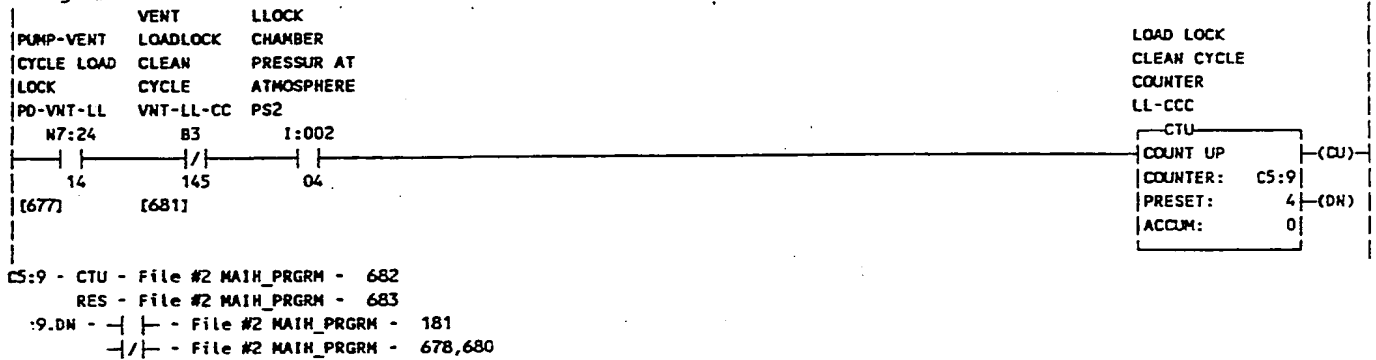
Rung #680



Rung #681



Rung #682



Rung #683

PUMP-VENT
CYCLE LOAD DOOR 1
LOCK OPEN
PD-VNT-LL DROP1S
N7:24 I:006

LOAD LOCK
CLEAN CYCLE
COUNTER
LL-CCC
CS:9
(RES)

14 01

[677]

CS:9 - CTU - File #2 MAIN_PRGRM - 682
CS:9.DN - | | - File #2 MAIN_PRGRM - 181
-|/| - File #2 MAIN_PRGRM - 678, 680

PAUSE
DISABLE
TS12
N7:16

4

[3]

Rung #684

PUMP DOWN
LOAD LOCK
PUSH BUTTON
PDLLPB
N7:3

AUTO
MODE
ENABLE
AUTO
N7:37

LOAD LOCK
DOOR 2
CLOSED
DRCL2S
I:006

CHAMBER =<250
MICRONS
PIR1
I:004

PIRANI
GUAGE 1
NO FAULT
PGNF1
I:004

VENT
LOAD LOCK
VNT_LL
N7:24

PUMP-VENT
CYCLE LOAD
LOCK
PD-VNT-LL
N7:24

LOAD LOCK
CHAMBER =<250
MICRONS
PIR1
I:004

PUMPDOWN
LOADLOCK
POLL
N7:24

15 11

[3]

[158]

PALLET PALLET
DETECTED DETECTED
CENTER RIGHT SIDE
LOADLOCK LOADLOCK
SENS5 SENS6
I:003 I:003

VENT AREA
1 ENABLE
VENT1E
N7:37

6

04

05

[410]

N7:24/15 - | | - File #2 MAIN_PRGRM - 68,167,675,685,686
-|/| - File #2 MAIN_PRGRM - 167,674,676
-(L)- File #2 MAIN_PRGRM - 684
-(U)- File #2 MAIN_PRGRM - 687

F:N7:21(X21) - BTW - File #2 MAIN_PRGRM - 2

Rung #685

PUMPDOWN
LOADLOCK
POLL
N7:24

15

[584]

ROUGH VALVE 1
OPEN DELAY
RV1OP_DLY

TON
TIMER ON DELAY (EN)
TIMER: T4:189
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 0

T4:189.DN - | | - File #2 MAIN_PRGRM - 167

418

Rung #491

MANUAL
CONTROL
CRYO GATE
10 OPEN
M-HV10-1
N7:4

MANUAL CRYO
GATE 10 OPEN
MCG10OP
N7:25

14

(L)
14

[3]
N7:25/14 - | | - File #2 MAIN_PRGRM - 133, 134, 494
-(U)- - File #2 MAIN_PRGRM - 492
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/5 - (L)- - File #2 MAIN_PRGRM - 492
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 10 CLOSE
MCG10CL
N7:27
(U)
5

Rung #492

MANUAL
CONTROL
CRYO GATE
10 CLOSE
M-HV10-0
N7:6

MANUAL CRYO
GATE 10 OPEN
MCG10OP
N7:25

5

(U)
14

[3]
N7:25/14 - | | - File #2 MAIN_PRGRM - 133, 134, 494
-(L)- - File #2 MAIN_PRGRM - 491
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/5 - (U)- - File #2 MAIN_PRGRM - 491
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 10 CLOSE
MCG10CL
N7:27
(L)
5

MANUAL
CONTROL
CRYO GATE
10THROTTLE
M-HV10-2
N7:5

9

[3]
PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]
COMPRESSOR
7 REGEN-
ERATION
PROGRAM
CYRGN7

83

327

[3:57]

419

Rung #493

MANUAL
CONTROL
CRYO GATE
10THROTTLE
M-HV10-2

N7:5

9

MANUAL CRYO
GATE 10
THROTTLE
MCG10TL

N7:26

(L)
9

[3]

N7:26/9 - | | - File #2 MAIN_PRGRM - 134,134
-(L)- - File #2 MAIN_PRGRM - 493
-(U)- - File #2 MAIN_PRGRM - 494

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #494

MANUAL
CONTROL
CRYO GATE
10 CLOSE
M-HV10-0

N7:6

5

MANUAL CRYO
GATE 10
THROTTLE
MCG10TL

N7:26

(U)
9

[3]

N7:26/9 - | | - File #2 MAIN_PRGRM - 134
-(L)- - File #2 MAIN_PRGRM - 493
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 10 OPEN
MCG10OP
N7:25

14

[492]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
7 REGEN-
ERATION
PROGRAM
CYRGN7

83

327

[3:57]

420

Rung #495

MANUAL
CONTROL
CRYO GATE
11 OPEN
M-HV11-1

N7:4

15

[3]

N7:25/15 - | | - File #2 MAIN_PRGRM - 135, 136, 498
-(U)- - File #2 MAIN_PRGRM - 496
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/6 - -(L)- - File #2 MAIN_PRGRM - 496
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 11 OPEN
MCG11OP
N7:25

(L)

15

MANUAL CRYO
GATE 11 CLOSE
MCG11CL

N7:27

(U)

6

Rung #496

MANUAL
CONTROL
CRYO GATE
11 CLOSE
M-HV11-0

N7:6

6

[3]

N7:25/15 - | | - File #2 MAIN_PRGRM - 135, 136, 498
-(L)- - File #2 MAIN_PRGRM - 495
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/6 - -(U)- - File #2 MAIN_PRGRM - 495
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CONTROL
CRYO GATE
11THROTTLE
M-HV11-2

N7:5

10

[3]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

COMPRESSOR
8 REGEN-
ERATION
PROGRAM
CYRGN8

83

328

[3:63]

MANUAL CRYO
GATE 11 OPEN
MCG11OP

N7:25

(U)

15

MANUAL CRYO
GATE 11 CLOSE
MCG11CL

N7:27

(L)

6

421

Rung #497

MANUAL
CONTROL
CRYO GATE
11 THROTTLE
M-HV11-2

N7:5

10

MANUAL CRYO
GATE 11
THROTTLE
MCG11TL

N7:26

(L)
10

[3]

N7:26/10 - | | - File #2 MAIN_PRGRM - 136,136

-(L)- - File #2 MAIN_PRGRM - 497

-(U)- - File #2 MAIN_PRGRM - 498

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #498

MANUAL
CONTROL
CRYO GATE
11 CLOSE
M-HV11-0

N7:6

6

MANUAL CRYO
GATE 11
THROTTLE
MCG11TL

N7:26

(U)

10

[3]

N7:26/10 - | | - File #2 MAIN_PRGRM - 136

-(L)- - File #2 MAIN_PRGRM - 497

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 11 OPEN
MCG11OP

N7:25

15

[496]

PREPARE FOR

AUTO RUN

>AUTO

N7:37

1

[162]

COMPRESSOR

8 REGEN-

ERATION

PROGRAM

CYRGN8

83

328

[3:63]

422

Rung #499

MANUAL
CONTROL
CRYO GATE
12 OPEN
M-HV12-1
N7:5

MANUAL CRYO
GATE 12 OPEN
MCG12OP
N7:26

(L)
0

(L)
0

[3]

N7:26/0 - | | - File #2 MAIN_PRGRM - 137, 138, 502
-(U)- - File #2 MAIN_PRGRM - 500
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/7 - -(L)- - File #2 MAIN_PRGRM - 500
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 12 CLOSE
MCG12CL
N7:27
(U)
7

Rung #500

MANUAL
CONTROL
CRYO GATE
12 CLOSE
M-HV12-0
N7:6

MANUAL CRYO
GATE 12 OPEN
MCG12OP
N7:26

(U)
0

(U)
0

[3]

N7:26/0 - | | - File #2 MAIN_PRGRM - 137, 138, 502
-(L)- - File #2 MAIN_PRGRM - 499
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/7 - -(U)- - File #2 MAIN_PRGRM - 499
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 12 CLOSE
MCG12CL
N7:27
(L)
7

MANUAL
CONTROL
CRYO GATE
12THROTTLE
M-HV12-2
N7:5

(L)
11

[3]

PREPARE FOR
AUTO RUN
>AUTO
N7:37

(L)
1

[162]

COMPRESSOR
7 REGEN-
ERATION
PROGRAM
YRGN7

(L)
83

(L)
327

[3:57]

423

Rung #501

MANUAL
CONTROL
CRYO GATE
12THROTTLE
M-HV12-2
N7:5

MANUAL CRYO
GATE 12
THROTTLE
MCG12TL

N7:26

11

(L)
11

[3]

N7:26/11 - | | - File #2 MAIN_PRGRM - 138,138

-(L)- - File #2 MAIN_PRGRM - 501

-(U)- - File #2 MAIN_PRGRM - 502

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #502

MANUAL
CONTROL
CRYO GATE
12 CLOSE
M-HV12-0
N7:6

MANUAL CRYO
GATE 12
THROTTLE
MCG12TL

N7:26

7

(U)
11

[3]

N7:26/11 - | | - File #2 MAIN_PRGRM - 138

-(L)- - File #2 MAIN_PRGRM - 501

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
GATE 12 OPEN
MCG12OP
N7:26

0

[500]

PREPARE FOR

AUTO RUN

>AUTO

N7:37

1

[162]

COMPRESSOR

7 REGEN-

ERATION

PROGRAM

CYRGN7

83

327

[3:57]

424

Rung #503

MANUAL CONTROL
ROUGH PUMP
VALVE 1 OPEN
M-RV1-1

N7:7

0

[3]

N7:28/0 - | | - File #2 MAIH_PRGRM - 167
-(U)- - File #2 MAIH_PRGRM - 508
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2
N7:33/3 - -(L)- - File #2 MAIH_PRGRM - 508
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL ROUGH
PUMP VALVE
1 OPEN
MRPV1OP
N7:28

(L)

0

MANUAL ROUGH
PUMP VALVE
1 CLOSE
MRPV1CL
N7:33

(U)

3

Rung #504

MANUAL CONTROL
ROUGH PUMP
VALVE 2 OPEN
M-RV2-1

N7:7

1

[3]

N7:28/1 - | | - File #2 MAIH_PRGRM - 56
-(U)- - File #2 MAIH_PRGRM - 509
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2
N7:33/4 - -(L)- - File #2 MAIH_PRGRM - 509
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL ROUGH
PUMP VALVE
2 OPEN
MRPV2OP
N7:28

(L)

1

MANUAL ROUGH
PUMP VALVE
2 CLOSE
MRPV2CL
N7:33

(U)

4

Rung #505

MANUAL CONTROL
ROUGH PUMP
VALVE 3 OPEN
M-RV3-1

N7:7

2

[3]

N7:28/2 - | | - File #2 MAIH_PRGRM - 57
-(U)- - File #2 MAIH_PRGRM - 510
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2
N7:33/5 - -(L)- - File #2 MAIH_PRGRM - 510
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL ROUGH
PUMP VALVE
3 OPEN
MRPV3OP
N7:28

(L)

2

MANUAL ROUGH
PUMP VALVE
3 CLOSE
MRPV3CL
N7:33

(U)

5

Rung #506

MANUAL CONTROL
ROUGH PUMP
VALVE 4 OPEN
M-RV4-1

N7:7

3

[3]

N7:28/3 - | | - File #2 MAIH_PRGRM - 58
-(U)- - File #2 MAIH_PRGRM - 511
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2
N7:33/6 - -(L)- - File #2 MAIH_PRGRM - 511
F:N7:21IX21 - BTW - File #2 MAIH_PRGRM - 2

MANUAL ROUGH
PUMP VALVE
4 OPEN
MRPV4OP
N7:28

(L)

3

MANUAL ROUGH
PUMP VALVE
4 CLOSE
MRPV4CL
N7:33

(U)

425

Rung #507

MANUAL CONTROL
ROUGH PUMP
VALVE 5 OPEN
M-RV5-1

N7:7

4

{3}

N7:28/4 - | | - File #2 MAIN_PRGRM - 340
-(U)- - File #2 MAIN_PRGRM - 512
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:33/7 - -(L)- - File #2 MAIN_PRGRM - 512
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL ROUGH
PUMP VALVE
5 OPEN
MRVP5OP
N7:28

(L)

4

MANUAL ROUGH
PUMP VALVE
5 CLOSE
MRPV5CL
N7:33

(U)

7

Rung #508

MANUAL
CONTROL
ROUGH PUMP
1 VALVE
CLOSE
M-RV1-0

N7:12

3

{3}

N7:28/0 - | | - File #2 MAIN_PRGRM - 167
-(L)- - File #2 MAIN_PRGRM - 503
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:33/3 - -(U)- - File #2 MAIN_PRGRM - 503
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

MANUAL ROUGH
PUMP VALVE
1 OPEN
MRPV1OP
N7:28

(U)

0

MANUAL ROUGH
PUMP VALVE
1 CLOSE
MRPV1CL
N7:33

(L)

3

Rung #509

MANUAL
CONTROL
ROUGH PUMP
2 VALVE
CLOSE
M-RV2-0

N7:12

4

{3}

N7:28/1 - | | - File #2 MAIN_PRGRM - 56
-(L)- - File #2 MAIN_PRGRM - 504
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:33/4 - -(U)- - File #2 MAIN_PRGRM - 504
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

MANUAL ROUGH
PUMP VALVE
2 OPEN
MRPV2OP
N7:28

(U)

1

MANUAL ROUGH
PUMP VALVE
2 CLOSE
MRPV2CL
N7:33

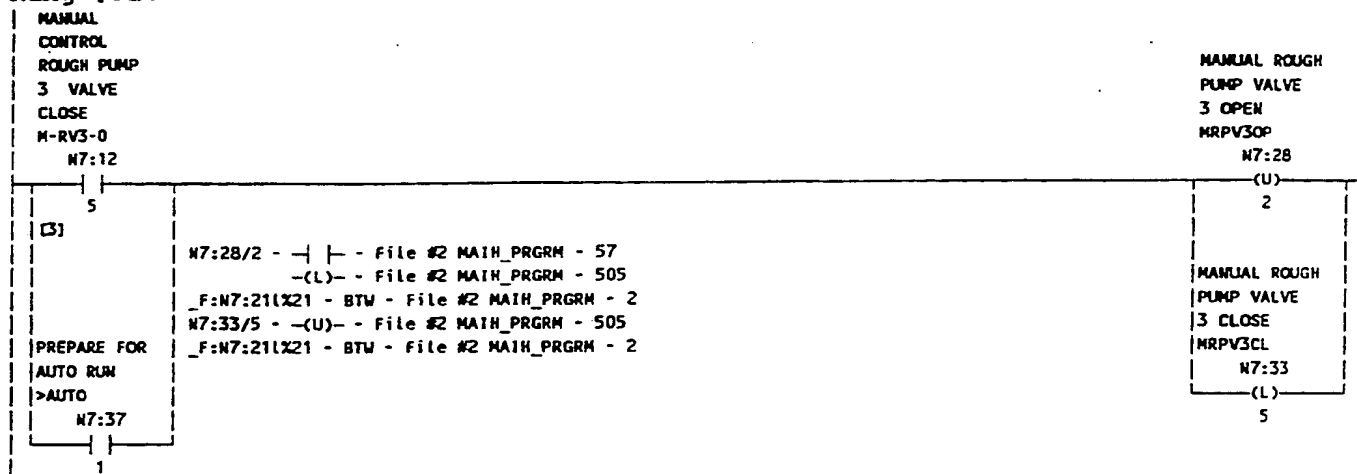
(L)

4

{162}

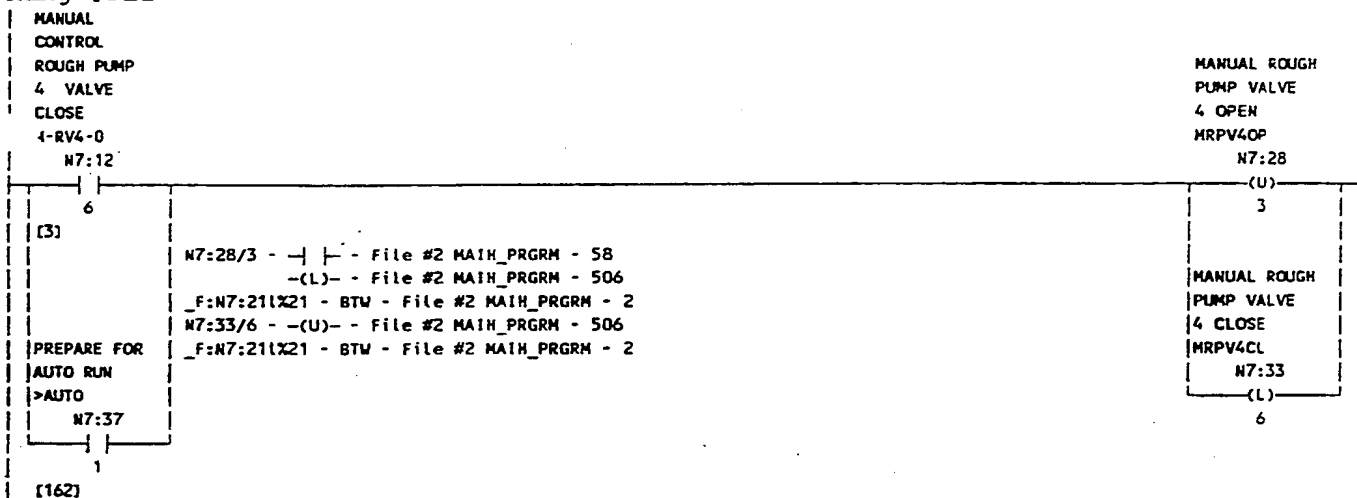
426

Rung #510



[162]

Rung #511



[162]

427

Rung #512

MANUAL
CONTROL
ROUGH PUMP
5 VALVE
CLOSE
M-RV5-0
N7:12

MANUAL ROUGH
PUMP VALVE
5 OPEN
MRVP5OP
N7:28

7

(U)

[3]

N7:28/4 - | | - File #2 MAIN_PRGRM - 340
-(L) - File #2 MAIN_PRGRM - 507
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:33/7 - -(U) - File #2 MAIN_PRGRM - 507
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL ROUGH
PUMP VALVE
5 CLOSE
MRPV5CL
N7:33

PREPARE FOR
AUTO RUN
>AUTO

N7:37

(L)

1

[162]

Rung #513

MANUAL
CONTROL
MOTOR 3
ON
M-MCON3
N7:2

MANUAL MOTOR
3 ON
MM3ON
N7:23

1

(L)

[3]

N7:23/1 - | | - File #2 MAIN_PRGRM - 185,187
-|/| - File #2 MAIN_PRGRM - 532
-(L) - File #2 MAIN_PRGRM - 513
-(U) - File #2 MAIN_PRGRM - 551
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #514

MANUAL
CONTROL
MOTOR 4
ON
M-MCON4
N7:2

MANUAL MOTOR
4 ON
MM4ON
N7:23

2

(L)

[3]

N7:23/2 - | | - File #2 MAIN_PRGRM - 190,192
-|/| - File #2 MAIN_PRGRM - 533
-(L) - File #2 MAIN_PRGRM - 514
-(U) - File #2 MAIN_PRGRM - 552
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #515

MANUAL
CONTROL
MOTOR 5
ON
M-MCON5
N7:2

MANUAL MOTOR
5 ON
MM5ON
N7:23

3

(L)

[3]

428

N7:23/3 - | | - File #2 MATH_PRGRM - 195,197
 -|/| - File #2 MATH_PRGRM - 534
 -(L)- File #2 MATH_PRGRM - 515
 -(U)- File #2 MATH_PRGRM - 553

F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #516

|MANUAL
 |CONTROL
 |MOTOR 6
 |ON
 |M-MCON6
 |N7:2

MANUAL MOTOR
 6 ON
 MM6ON

N7:23

(L)

4

[3]

N7:23/4 - | | - File #2 MATH_PRGRM - 218,220
 -|/| - File #2 MATH_PRGRM - 535
 -(L)- File #2 MATH_PRGRM - 516
 -(U)- File #2 MATH_PRGRM - 554

F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #517

|MANUAL
 |CONTROL
 |MOTOR 7
 |ON
 |M-MCON7
 |N7:2

MANUAL MOTOR
 7 ON
 MM7ON

N7:23

(L)

5

[3]

N7:23/5 - | | - File #2 MATH_PRGRM - 231,233
 -|/| - File #2 MATH_PRGRM - 536
 -(L)- File #2 MATH_PRGRM - 517
 -(U)- File #2 MATH_PRGRM - 555

F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #518

|MANUAL
 |CONTROL
 |MOTOR 8
 |ON
 |M-MCON8
 |N7:2

MANUAL MOTOR
 8 ON
 MM8ON

N7:23

(L)

6

[3]

N7:23/6 - | | - File #2 MATH_PRGRM - 249
 -|/| - File #2 MATH_PRGRM - 537
 -(L)- File #2 MATH_PRGRM - 518
 -(U)- File #2 MATH_PRGRM - 556

F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #519

|MANUAL
 |CONTROL
 |MOTOR 9
 |ON
 |M-MCON9
 |N7:2

MANUAL MOTOR
 9 ON
 MM9ON

N7:23

(L)

7

[3]

N7:23/7 - | | - File #2 MATH_PRGRM - 253,255
 -|/| - File #2 MATH_PRGRM - 538

429

-(L)- - File #2 MAIN_PRGRM - 519

-(U)- - File #2 MAIN_PRGRM - 557

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #520

|MANUAL

|CONTROL

|MOTOR 10

|ON

|M-MCON10

|N7:2

|8

|[3]

N7:23/8 - | | - File #2 MAIN_PRGRM - 258,260

-|/| - File #2 MAIN_PRGRM - 539

-(L)- - File #2 MAIN_PRGRM - 520

-(U)- - File #2 MAIN_PRGRM - 558

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #521

|MANUAL

|CONTROL

|MOTOR 11

|ON

|M-MCON11

|N7:2

|9

|[3]

N7:23/9 - | | - File #2 MAIN_PRGRM - 263,265

-|/| - File #2 MAIN_PRGRM - 540

-(L)- - File #2 MAIN_PRGRM - 521

-(U)- - File #2 MAIN_PRGRM - 559

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #522

|MANUAL

|CONTROL

|MOTOR 12

|ON

|M-MCON12

|N7:2

|10

|[3]

N7:23/10 - | | - File #2 MAIN_PRGRM - 281

-|/| - File #2 MAIN_PRGRM - 541

-(L)- - File #2 MAIN_PRGRM - 522

-(U)- - File #2 MAIN_PRGRM - 560

_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #523

|MANUAL

|CONTROL

|MOTOR 13

|ON

|M-MCON13

|N7:2

|11

|[3]

N7:23/11 - | | - File #2 MAIN_PRGRM - 285,287

-|/| - File #2 MAIN_PRGRM - 542

-(L)- - File #2 MAIN_PRGRM - 523

-(U)- - File #2 MAIN_PRGRM - 561

MANUAL MOTOR

10 ON

MM10ON

N7:23

(L)

8

MANUAL MOTOR

11 ON

MM11ON

N7:23

(L)

9

MANUAL MOTOR

12 ON

MM12ON

N7:23

(L)

10

MANUAL MOTOR

13 ON

MM13ON

N7:23

(L)

11

430

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #524

|MANUAL

|CONTROL

|MOTOR 14

|ON

|M-MCON14

N7:2

|

12

| [3]

N7:23/12 - | | - File #2 MATH_PRGRM - 290,292

-|/| - File #2 MATH_PRGRM - 543

-(L)- File #2 MATH_PRGRM - 524

-(U)- File #2 MATH_PRGRM - 562

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #525

|MANUAL

|CONTROL

|MOTOR 15

|ON

|M-MCON15

N7:2

|

13

| [3]

N7:23/13 - | | - File #2 MATH_PRGRM - 295,297

-|/| - File #2 MATH_PRGRM - 544

-(L)- File #2 MATH_PRGRM - 525

-(U)- File #2 MATH_PRGRM - 563

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #526

|MANUAL

|CONTROL

|MOTOR 16

|ON

|M-MCON16

N7:2

|

14

| [3]

N7:23/14 - | | - File #2 MATH_PRGRM - 306

-|/| - File #2 MATH_PRGRM - 545

-(L)- File #2 MATH_PRGRM - 526

-(U)- File #2 MATH_PRGRM - 564

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

Rung #527

|MANUAL

|CONTROL

|MOTOR 17

|ON

|M-MCON17

N7:2

|

15

| [3]

N7:23/15 - | | - File #2 MATH_PRGRM - 310,312

-|/| - File #2 MATH_PRGRM - 546

-(L)- File #2 MATH_PRGRM - 527

-(U)- File #2 MATH_PRGRM - 565

_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MANUAL MOTOR

14 ON

MM14ON

N7:23

(L)

12

MANUAL MOTOR

15 ON

MM15ON

N7:23

(L)

13

MANUAL MOTOR

16 ON

MM16ON

N7:23

(L)

14

MANUAL MOTOR

17 ON

MM17ON

N7:23

(L)

15

431

Rung #528

MANUAL
CONTROL
MOTOR 18
ON
M-MCON18
N7:3

MANUAL MOTOR
18 ON
MM18ON
N7:24

0 (L) 0

[3]

N7:24/0 - | | - File #2 MAIN_PRGRM - 315,317
-|/| - File #2 MAIN_PRGRM - 547
-(L)- - File #2 MAIN_PRGRM - 528
-(U)- - File #2 MAIN_PRGRM - 566

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #529

MANUAL
CONTROL
MOTOR 19
ON
M-MCON19
N7:3

MANUAL MOTOR
19 ON
MM19ON
N7:24

1 (L) 1

[3]

N7:24/1 - | | - File #2 MAIN_PRGRM - 320,322
-|/| - File #2 MAIN_PRGRM - 548
-(L)- - File #2 MAIN_PRGRM - 529
-(U)- - File #2 MAIN_PRGRM - 567

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #530

MANUAL
CONTROL
MOTOR 20
ON
M-MCON20
N7:3

MANUAL MOTOR
20 ON
MM20ON
N7:24

2 (L) 2

[3]

N7:24/2 - | | - File #2 MAIN_PRGRM - 331,333
-|/| - File #2 MAIN_PRGRM - 549,550
-(L)- - File #2 MAIN_PRGRM - 530
-(U)- - File #2 MAIN_PRGRM - 568

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #531

MANUAL
CONTROL
MOTOR 21
ON
MCON21
N7:3

MANUAL MOTOR
21 ON
MM21ON
N7:24

3 (L) 3

[3]

N7:24/3 - | | - File #2 MAIN_PRGRM - 355,357
-(L)- - File #2 MAIN_PRGRM - 531
-(U)- - File #2 MAIN_PRGRM - 569

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

432

Rung #532

MANUAL MOTOR

3 ON

MM3ON

N7:23

|/|

1

[S13]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #533

MANUAL MOTOR

4 ON

MM4ON

N7:23

|/|

2

[S14]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #534

MANUAL MOTOR

5 ON

MM5ON

N7:23

|/|

3

[S15]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #535

MANUAL MOTOR

6 ON

MM6ON

N7:23

|/|

4

[S16]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #536

MANUAL MOTOR

7 ON

MM7ON

N7:23

|/|

5

[S17]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #537

MANUAL MOTOR

8 ON

MM8ON

N7:23

|/|

6

[S18]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL MOTOR

3 OFF

MM3OFF

N7:21

()

3

MANUAL MOTOR

4 OFF

MM4OFF

N7:21

()

4

MANUAL MOTOR

5 OFF

MM5OFF

N7:21

()

5

MANUAL MOTOR

6 OFF

MM6OFF

N7:21

()

6

MANUAL MOTOR

7 OFF

MM7OFF

N7:21

()

7

MANUAL MOTOR

8 OFF

MM8OFF

N7:21

()

8

433

Rung #538

MANUAL MOTOR

9 ON

MM9ON

N7:23

|/|
7

MANUAL MOTOR

9 OFF

MM9OFF

N7:21

()
9

[S19]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #539

MANUAL MOTOR

10 ON

MM10ON

N7:23

|/|
8

MANUAL MOTOR

10 OFF

MM10OFF

N7:21

()
10

[S20]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #540

MANUAL MOTOR

11 ON

MM11ON

N7:23

|/|
9

MANUAL MOTOR

11 OFF

MM11OFF

N7:21

()
11

[S21]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #541

MANUAL MOTOR

12 ON

MM12ON

N7:23

|/|
10

MANUAL MOTOR

12 OFF

MM12OFF

N7:21

()
12

[S22]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #542

MANUAL MOTOR

13 ON

MM13ON

N7:23

|/|
11

MANUAL MOTOR

13 OFF

MM13OFF

N7:21

()
13

[S23]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #543

MANUAL MOTOR

14 ON

MM14ON

N7:23

|/|
12

MANUAL MOTOR

14 OFF

MM14OFF

N7:21

()
14

[S24]

N7:21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

436

Rung #544

MANUAL MOTOR	MANUAL MOTOR
15 ON	15 OFF
MM15ON	MM15OFF
N7:23	N7:21
/	/
13	15

[525]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #545

MANUAL MOTOR	MANUAL MOTOR
16 ON	16 OFF
MM16ON	MM16OFF
N7:23	N7:22
/	/
14	0

[526]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #546

MANUAL MOTOR	MANUAL MOTOR
17 ON	17 OFF
MM17ON	MM17OFF
N7:23	N7:22
/	/
15	1

[527]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #547

MANUAL MOTOR	MANUAL MOTOR
18 ON	18 OFF
MM18ON	MM18OFF
N7:24	N7:22
/	/
0	2

[528]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #548

MANUAL MOTOR	MANUAL MOTOR
19 ON	19 OFF
MM19ON	MM19OFF
N7:24	N7:22
/	/
1	3

[529]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #549

MANUAL MOTOR	MANUAL MOTOR
20 ON	20 OFF
MM20ON	MM20OFF
N7:24	N7:22
/	/
2	4

[530]

F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #550

MANUAL MOTOR	MANUAL MOTOR
20 ON	21 OFF
MM20ON	MM21OFF
N7:24	N7:22
/	/
2	5

[568]

435

F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #551

MANUAL
CONTROL
MOTOR 3
OFF
M-MCOF3
N7:0

MANUAL MOTOR
3 ON
MM3ON
N7:23

(U) 1

(3)

N7:23/1 - \neg \neg - File #2 MAIN_PRGRM - 185, 187
 \neg \neg - File #2 MAIN_PRGRM - 532
 \neg (L)- - File #2 MAIN_PRGRM - 513
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

(162)

Rung #552

MANUAL
CONTROL
MOTOR 4
OFF
M-MCOF4
N7:0

MANUAL MOTOR
4 ON
MM4ON
N7:23

(U) 2

(3)

N7:23/2 - \neg \neg - File #2 MAIN_PRGRM - 190, 192
 \neg \neg - File #2 MAIN_PRGRM - 533
 \neg (L)- - File #2 MAIN_PRGRM - 514
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

(162)

436

Rung #553

MANUAL
CONTROL
MOTOR 5
OFF
M-MCOF5
N7:0

MANUAL MOTOR
5 ON
MM5ON
N7:23

5

(U)
3

[3]

N7:23/3 - | | - File #2 MATH_PRGRM - 195, 197
-|/| - File #2 MATH_PRGRM - 534
-(L)- - File #2 MATH_PRGRM - 515
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

Rung #554

MANUAL
CONTROL
MOTOR 6
OFF
M-MCOF6
N7:0

MANUAL MOTOR
6 ON
MM6ON
N7:23

6

(U)
4

[3]

N7:23/4 - | | - File #2 MATH_PRGRM - 218, 220
-|/| - File #2 MATH_PRGRM - 535
-(L)- - File #2 MATH_PRGRM - 516
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

Rung #555

MANUAL
CONTROL
MOTOR 7
OFF
M-MCOF7
N7:0

MANUAL MOTOR
7 ON
MM7ON
N7:23

7

(U)
5

[3]

N7:23/5 - | | - File #2 MATH_PRGRM - 231, 233
-|/| - File #2 MATH_PRGRM - 536
-(L)- - File #2 MATH_PRGRM - 517
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

437

Rung #556

MANUAL
CONTROL
MOTOR 8
OFF
M-MCOF8
N7:0

MANUAL MOTOR
8 ON
MM8ON
N7:23

8

[3]

N7:23/6 - | | - File #2 MAIN_PRGRM - 249
 -|/| - File #2 MAIN_PRGRM - 537
 -(L)- - File #2 MAIN_PRGRM - 518
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

Rung #557

MANUAL
CONTROL
MOTOR 9
OFF
M-MCOF9
N7:0

MANUAL MOTOR
9 ON
MM9ON
N7:23

9

[3]

N7:23/7 - | | - File #2 MAIN_PRGRM - 253, 255
 -|/| - File #2 MAIN_PRGRM - 538
 -(L)- - File #2 MAIN_PRGRM - 519
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

Rung #558

MANUAL
CONTROL
MOTOR 10
OFF
M-MCOF10
N7:0

MANUAL MOTOR
10 ON
MM10ON
N7:23

10

[3]

N7:23/8 - | | - File #2 MAIN_PRGRM - 258, 260
 -|/| - File #2 MAIN_PRGRM - 539
 -(L)- - File #2 MAIN_PRGRM - 520
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

438

Rung #559

MANUAL
CONTROL
MOTOR 11
OFF
M-MCOF11
N7:0

MANUAL MOTOR
11 ON
MM11ON
N7:23

N7:0
11

(U)
9

[3]

N7:23/9 - | | - File #2 MATH_PRGRM - 263, 265
- | | - File #2 MATH_PRGRM - 540
-(L)- - File #2 MATH_PRGRM - 521
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

Rung #560

MANUAL
CONTROL
MOTOR 12
OFF
M-MCOF12
N7:0

MANUAL MOTOR
12 ON
MM12ON
N7:23

N7:0
12

(U)
10

[3]

N7:23/10 - | | - File #2 MATH_PRGRM - 281
- | | - File #2 MATH_PRGRM - 541
-(L)- - File #2 MATH_PRGRM - 522
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

Rung #561

MANUAL
CONTROL
MOTOR 13
OFF
M-MCOF13
N7:0

MANUAL MOTOR
13 ON
MM13ON
N7:23

N7:0
13

(U)
11

[3]

N7:23/11 - | | - File #2 MATH_PRGRM - 285, 287
- | | - File #2 MATH_PRGRM - 542
-(L)- - File #2 MATH_PRGRM - 523
_F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

439

Rung #562

MANUAL
CONTROL
MOTOR 14
OFF
M-MCOF14
N7:0

MANUAL MOTOR
14 ON
MM14ON
N7:23

14

[3]

N7:23/12 - | | - File #2 MAIN_PRGRM - 290, 292
- | | - File #2 MAIN_PRGRM - 543
-(L)- - File #2 MAIN_PRGRM - 524
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

Rung #563

MANUAL
CONTROL
MOTOR 15
OFF
M-MCOF15
N7:0

MANUAL MOTOR
15 ON
MM15ON
N7:23

15

[3]

N7:23/13 - | | - File #2 MAIN_PRGRM - 295, 297
- | | - File #2 MAIN_PRGRM - 544
-(L)- - File #2 MAIN_PRGRM - 525
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

Rung #564

MANUAL
CONTROL
MOTOR 16
OFF
M-MCOF16
N7:1

MANUAL MOTOR
16 ON
MM16ON
N7:23

0

[3]

N7:23/14 - | | - File #2 MAIN_PRGRM - 306
- | | - File #2 MAIN_PRGRM - 545
-(L)- - File #2 MAIN_PRGRM - 526
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[162]

440

Rung #565

MANUAL
CONTROL
MOTOR 17
OFF
M-MCOF17
N7:1

MANUAL MOTOR
17 ON
MM17ON
N7:23

(U)
15

[3]

N7:23/15 - | | - File #2 MAIN_PRGRM - 310, 312
- | | - File #2 MAIN_PRGRM - 546
-(L)- - File #2 MAIN_PRGRM - 527
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

Rung #566

MANUAL
CONTROL
MOTOR 18
OFF
M-MCOF18
N7:1

MANUAL MOTOR
18 ON
MM18ON
N7:24

(U)
0

[3]

N7:24/0 - | | - File #2 MAIN_PRGRM - 315, 317
- | | - File #2 MAIN_PRGRM - 547
-(L)- - File #2 MAIN_PRGRM - 528
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

[162]

Rung #567

MANUAL
CONTROL
MOTOR 19
OFF
M-MCOF19
N7:1

MANUAL MOTOR
19 ON
MM19ON
N7:24

(U)
1

[3]

N7:24/1 - | | - File #2 MAIN_PRGRM - 320, 322
- | | - File #2 MAIN_PRGRM - 548
-(L)- - File #2 MAIN_PRGRM - 529
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

PREPARE FOR
AUTO RUN
>AUTO
N7:37

1

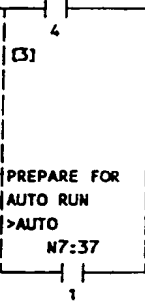
[162]

441

Rung #568

MANUAL
CONTROL
MOTOR 20
OFF
M-MCOF20
N7:1

MANUAL MOTOR
20 ON
MM20ON
N7:24



N7:24/2 - | | - File #2 MAIN_PRGRM - 331, 333
- | | - File #2 MAIN_PRGRM - 549, 550
-(L)- - File #2 MAIN_PRGRM - 530
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

(U)
2

[162]
Rung #569

MANUAL
CONTROL
MOTOR 21
OFF
M-MCOF21
N7:1

MANUAL MOTOR
21 ON
MM21ON
N7:24



N7:24/3 - | | - File #2 MAIN_PRGRM - 355, 357
-(L)- - File #2 MAIN_PRGRM - 531
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

(U)
3

[162]

442

Rung #570

MOTOR 3
REVERSE
ENABLE
M3RE

N7:19

2

(3)

B3/103 - | | - File #2 MATH_PRGRM - 187
 -|/| - File #2 MATH_PRGRM - 185
 -(U)- - File #2 MATH_PRGRM - 589
 N7:40/2 - -(U)- - File #2 MATH_PRGRM - 589
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2
 N7:34/15 - -(L)- - File #2 MATH_PRGRM - 589
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MOTOR 3
REVERSE
M3R

B3

(L)

103

MANUAL
MOTOR 3
REVERSE
ENABLE
M3RE

N7:40

(L)

2

MANUAL
MOTOR 3
REVERSE
DISABLE
M3RD

N7:34

(U)

15

Rung #571

MOTOR 4
REVERSE
ABLE
M4RE

N7:19

3

(3)

B3/104 - | | - File #2 MATH_PRGRM - 192
 -|/| - File #2 MATH_PRGRM - 190
 -(U)- - File #2 MATH_PRGRM - 590
 N7:40/3 - -(U)- - File #2 MATH_PRGRM - 590
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2
 N7:35/0 - -(L)- - File #2 MATH_PRGRM - 590
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MOTOR 4
REVERSE
M4R

B3

(L)

104

MANUAL
MOTOR 4
REVERSE
ENABLE
M4RE

N7:40

(L)

3

MANUAL
MOTOR 4
REVERSE
DISABLE
M4RD

N7:35

(U)

0

443

Rung #572

MOTOR 5
REVERSE
ENABLE
MSRE

N7:19

4

(3)

B3/105 - | | - File #2 MAIN_PRGRM - 197
 -|/| - File #2 MAIN_PRGRM - 195
 -(U)- - File #2 MAIN_PRGRM - 591
 N7:40/4 - -(U)- - File #2 MAIN_PRGRM - 591
 _F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/1 - -(L)- - File #2 MAIN_PRGRM - 591
 _F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 5
REVERSE
MSR

B3

-(L)-

105

MANUAL
MOTOR 5
REVERSE
ENABLE
MSRE

N7:40

-(L)-

4

MANUAL
MOTOR 5
REVERSE
DISABLE
MSRD

N7:35

-(U)-

1

Rung #573

MOTOR 6
REVERSE
ENABLE
MSRE

N7:19

5

(3)

B3/106 - | | - File #2 MAIN_PRGRM - 220
 -|/| - File #2 MAIN_PRGRM - 218
 -(U)- - File #2 MAIN_PRGRM - 592
 N7:40/5 - -(U)- - File #2 MAIN_PRGRM - 592
 _F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/2 - -(L)- - File #2 MAIN_PRGRM - 592
 _F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 6
REVERSE
MSR

B3

-(L)-

106

MANUAL
MOTOR 6
REVERSE
ENABLE
MSRE

N7:40

-(L)-

5

MANUAL
MOTOR 6
REVERSE
DISABLE
MSRD

N7:35

-(U)-

2

444

Rung #574

MOTOR 7		MOTOR 7
REVERSE		REVERSE
ENABLE		ENABLE
M7RE		M7R
N7:19		B3
6		(L)
[3]		107
B3/107 - - File #2 MAIN_PRGRM - 233		MANUAL
/ - File #2 MAIN_PRGRM - 231		MOTOR 7
-(U)- File #2 MAIN_PRGRM - 593		REVERSE
N7:40/6 - -(U)- File #2 MAIN_PRGRM - 593		ENABLE
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2		M7RE
N7:35/3 - -(L)- File #2 MAIN_PRGRM - 593		N7:40
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2		(L)
		6
		MANUAL
		MOTOR 7
		REVERSE
		DISABLE
		M7RD
		N7:35
		(U)
		3

Rung #575

MOTOR 8		MOTOR 8
REVERSE		REVERSE
ENABLE		ENABLE
M8RE		M8R
N7:19		B3
7		(L)
[3]		108
B3/108 - - File #2 MAIN_PRGRM - 249		MANUAL
/ - File #2 MAIN_PRGRM - 249		MOTOR 8
-(U)- File #2 MAIN_PRGRM - 594		REVERSE
N7:40/7 - -(U)- File #2 MAIN_PRGRM - 594		ENABLE
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2		M8RE
N7:35/4 - -(L)- File #2 MAIN_PRGRM - 594		N7:40
_F:N7:21LX21 - BTW - File #2 MAIN_PRGRM - 2		(L)
		7
		MANUAL
		MOTOR 8
		REVERSE
		DISABLE
		M8RD
		N7:35
		(U)
		4

445

Rung #576

MOTOR 9
REVERSE
ENABLE
M9RE

N7:19

8

(3)

B3/109 - | | - File #2 MAIN_PRGRM - 255
 -|/| - File #2 MAIN_PRGRM - 253
 -(U)- - File #2 MAIN_PRGRM - 595
 N7:40/8 - -(U)- - File #2 MAIN_PRGRM - 595
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/5 - -(L)- - File #2 MAIN_PRGRM - 595
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 9
REVERSE
M9R

B3

(L)

109

MANUAL
MOTOR 9
REVERSE
ENABLE
M9RE

N7:40

(L)

8

MANUAL
MOTOR 9
REVERSE
DISABLE
M9RD

N7:35

(U)

5

Rung #577

MOTOR 10
REVERSE
ENABLE
M10RE

N7:19

9

(3)

B3/110 - | | - File #2 MAIN_PRGRM - 260
 -|/| - File #2 MAIN_PRGRM - 258
 -(U)- - File #2 MAIN_PRGRM - 596
 N7:40/9 - -(U)- - File #2 MAIN_PRGRM - 596
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/6 - -(L)- - File #2 MAIN_PRGRM - 596
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 10
REVERSE
M10R

B3

(L)

110

MANUAL
MOTOR 10
REVERSE
ENABLE
M10RE

N7:40

(L)

9

MANUAL
MOTOR 10
REVERSE
DISABLE
M10RD

N7:35

(L)

6

446

Rung #578

MOTOR 11
 REVERSE
 ENABLE
 M11RE
 N7:19

10

[3]

B3/111 - | | - File #2 MATH_PRGRM - 265
 -|/| - File #2 MATH_PRGRM - 263
 -(U)- - File #2 MATH_PRGRM - 597
 N7:40/10 - -(U)- - File #2 MATH_PRGRM - 597
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2
 N7:35/7 - -(L)- - File #2 MATH_PRGRM - 597
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MOTOR 11
 REVERSE
 M11R

B3

(L)

111

MANUAL
 MOTOR 11
 REVERSE
 ENABLE
 M11RE

N7:40

(L)

10

MANUAL
 MOTOR 11
 REVERSE
 DISABLE
 M11RD

N7:35

(U)

7

Rung #579

MOTOR 12
 REVERSE
 ENABLE
 M12RE
 N7:19

11

[3]

B3/112 - | | - File #2 MATH_PRGRM - 281
 -|/| - File #2 MATH_PRGRM - 281
 -(U)- - File #2 MATH_PRGRM - 598
 N7:40/11 - -(U)- - File #2 MATH_PRGRM - 598
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2
 N7:35/8 - -(L)- - File #2 MATH_PRGRM - 598
 _F:N7:211X21 - BTW - File #2 MATH_PRGRM - 2

MOTOR 12
 REVERSE
 M12R

B3

(L)

112

MANUAL
 MOTOR 12
 REVERSE
 ENABLE
 M12RE

N7:40

(L)

11

MANUAL
 MOTOR 12
 REVERSE
 DISABLE
 M12RD

N7:35

(U)

8

447

Rung #580

MOTOR 13

REVERSE

ENABLE

M13RE

N7:19

12

[3]

B3/113 - | | - File #2 MAIN_PRGRM - 287
 -|/| - File #2 MAIN_PRGRM - 285
 -(U)- - File #2 MAIN_PRGRM - 599
 N7:40/12 - -(U)- - File #2 MAIN_PRGRM - 599
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/9 - -(L)- - File #2 MAIN_PRGRM - 599
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 13

REVERSE

M13R

B3

(L)

113

MANUAL

MOTOR 13

REVERSE

ENABLE

M13RE

N7:40

(L)

12

MANUAL

MOTOR 13

REVERSE

DISABLE

M13RD

N7:35

(U)

9

Rung #581

MOTOR 14

REVERSE

ENABLE

M14RE

N7:19

13

[3]

B3/114 - | | - File #2 MAIN_PRGRM - 292
 -|/| - File #2 MAIN_PRGRM - 290
 -(U)- - File #2 MAIN_PRGRM - 600
 N7:40/13 - -(U)- - File #2 MAIN_PRGRM - 600
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
 N7:35/10 - -(L)- - File #2 MAIN_PRGRM - 600
 _F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MOTOR 14

REVERSE

M14R

B3

(L)

114

MANUAL

MOTOR 14

REVERSE

ENABLE

M14RE

N7:40

(L)

13

MANUAL

MOTOR 14

REVERSE

DISABLE

M14RD

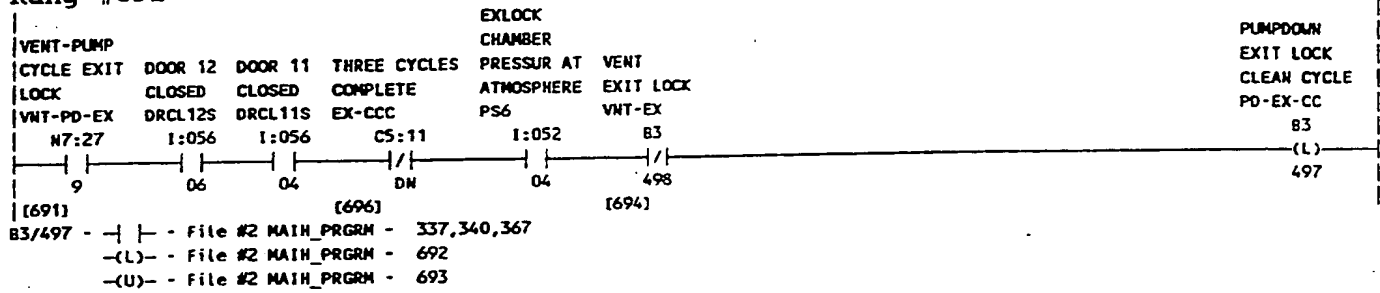
N7:35

(U)

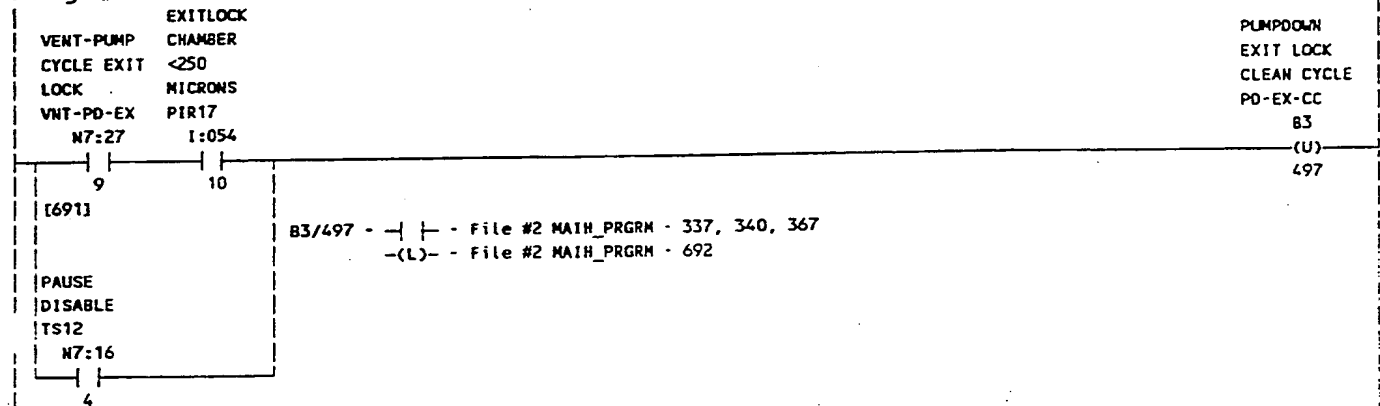
10

448

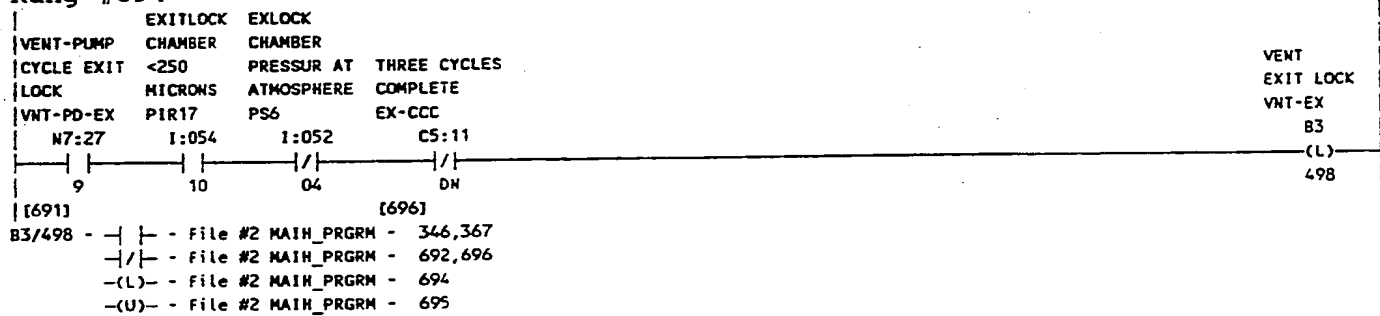
Rung #692



Rung #693

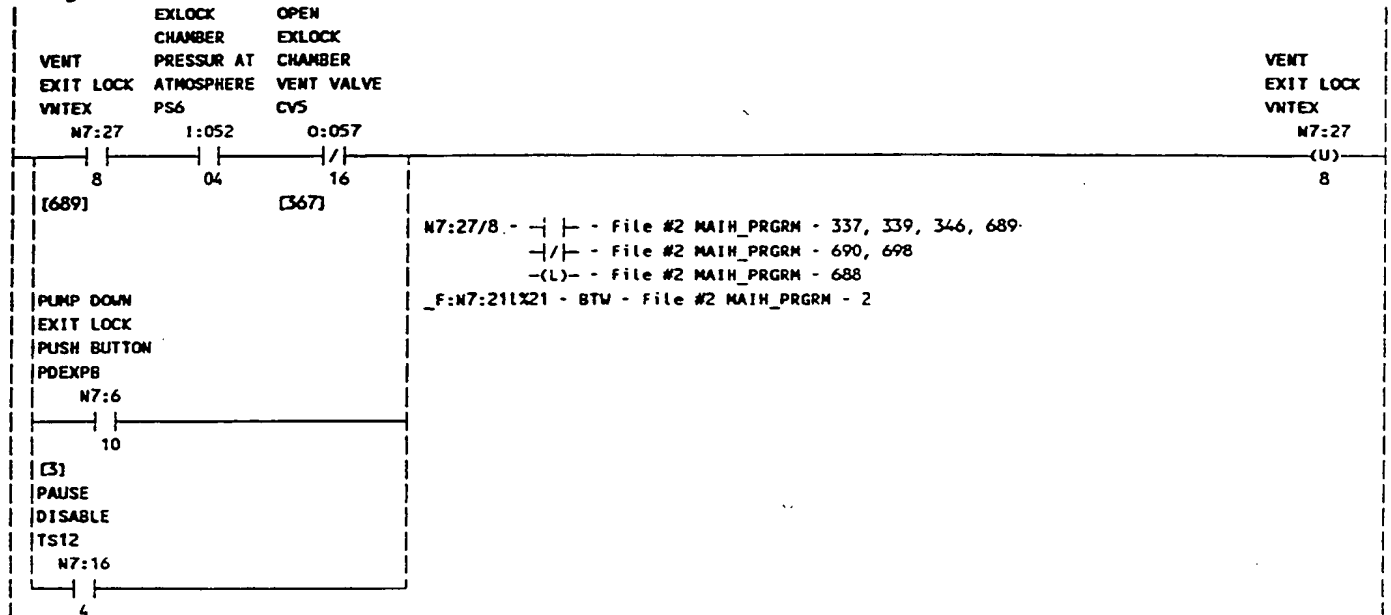


Rung #694

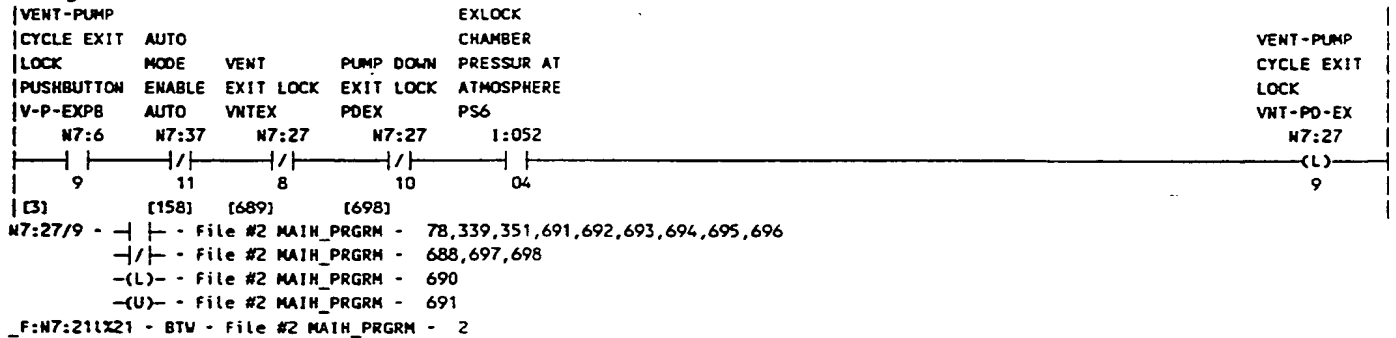


449

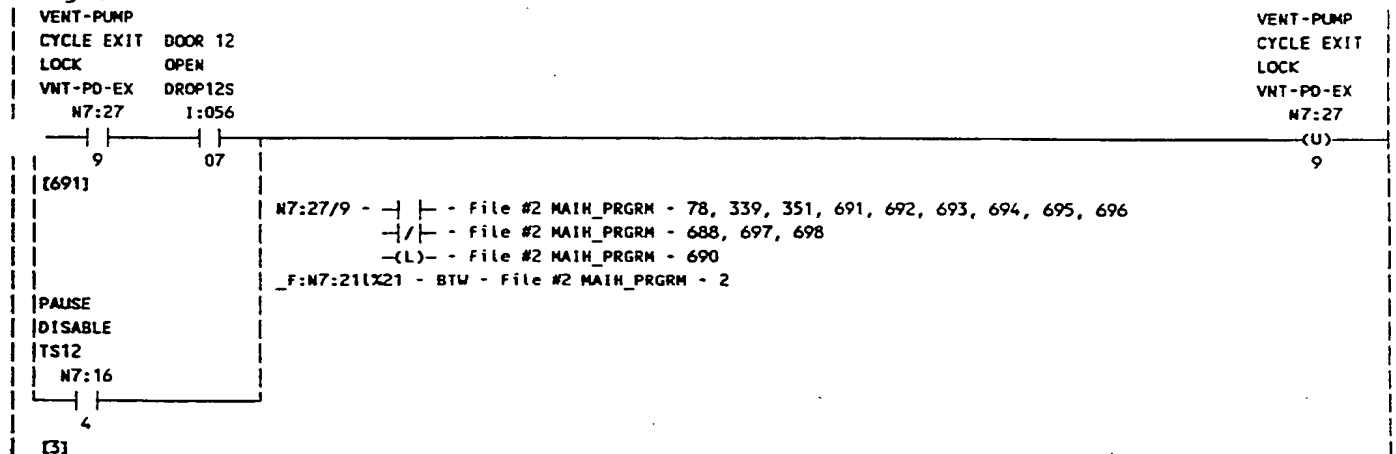
Rung #689



Rung #690

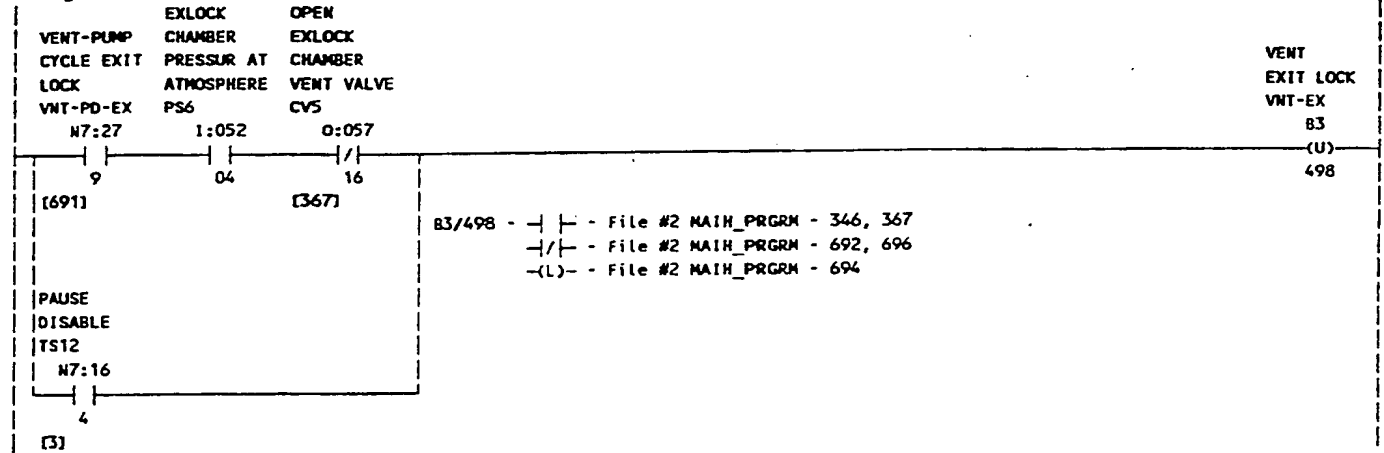


Rung #691

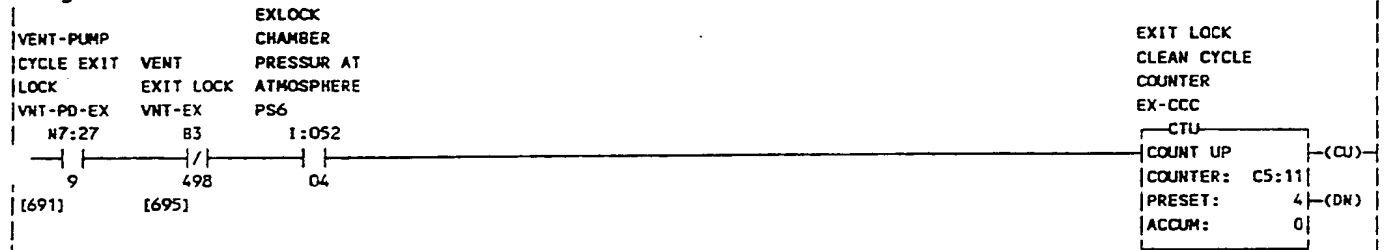


450

Rung #695



Rung #696



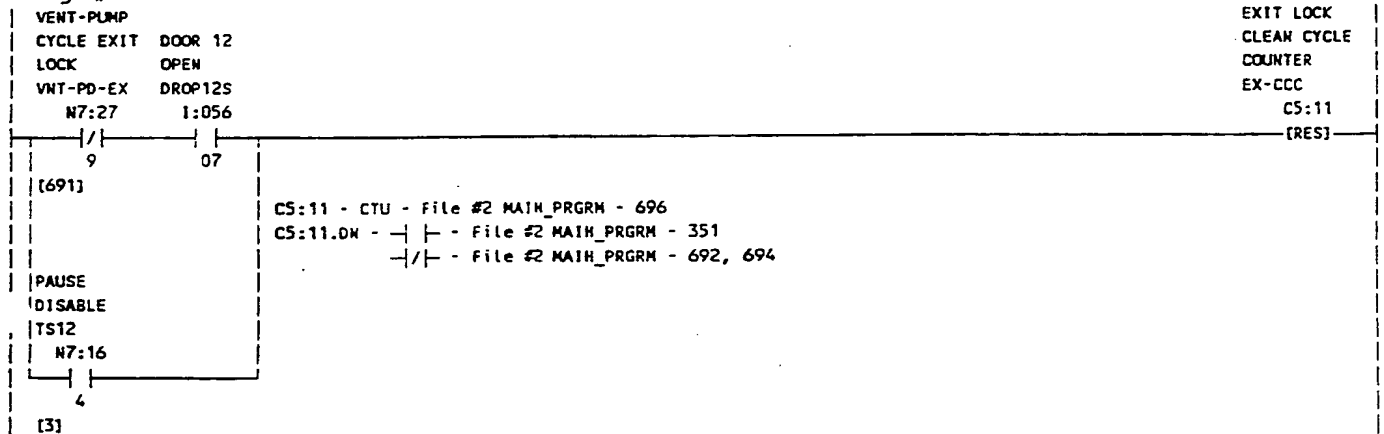
C5:11 - CTU - File #2 MAIN_PRGRM - 696

RES - File #2 MAIN_PRGRM - 697

C5:11.DN - | | - File #2 MAIN_PRGRM - 351

-|/| - File #2 MAIN_PRGRM - 692, 694

Rung #697



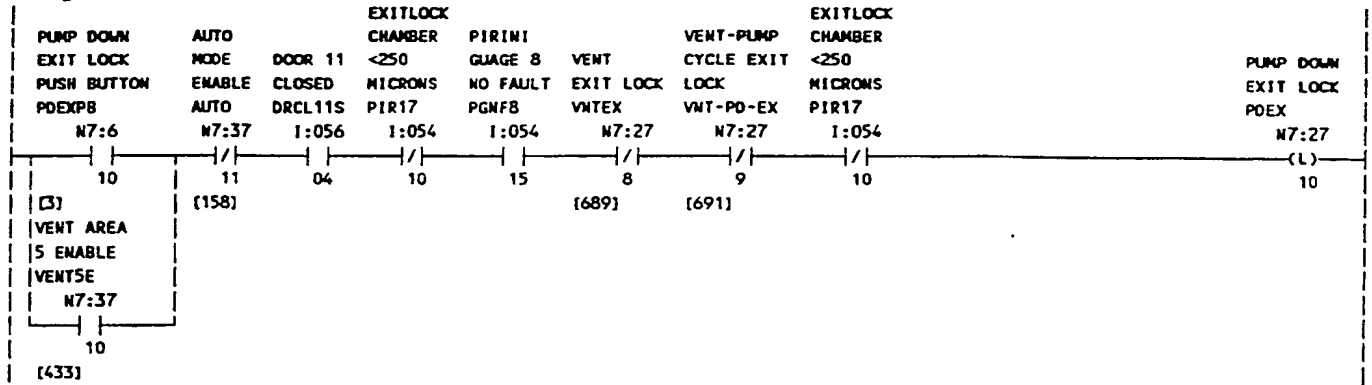
C5:11 - CTU - File #2 MAIN_PRGRM - 696

C5:11.DN - | | - File #2 MAIN_PRGRM - 351

-|/| - File #2 MAIN_PRGRM - 692, 694

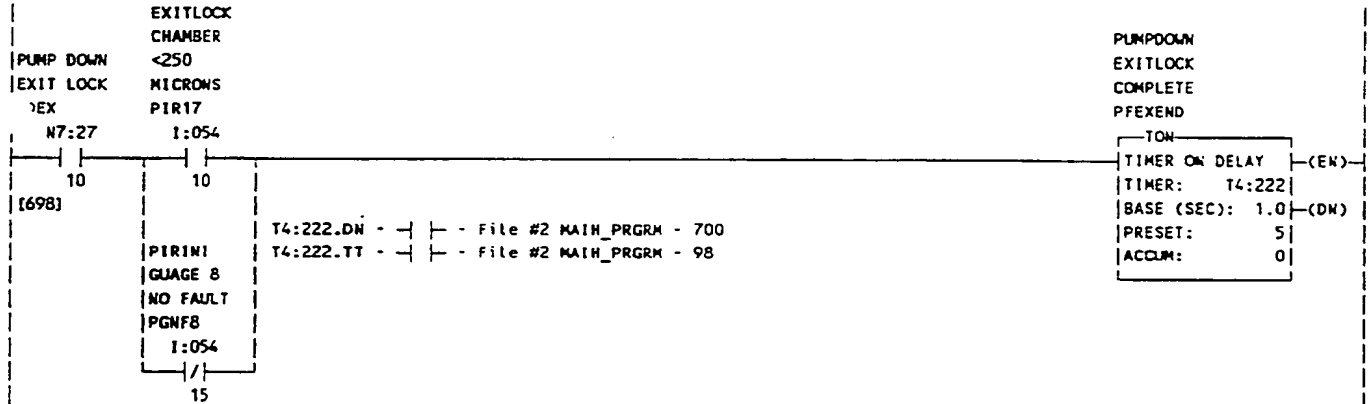
451

Rung #698



N7:27/10 - | | - File #2 MAIN_PRGRM - 78,340,699
 -|/| - File #2 MAIN_PRGRM - 109,688,690
 -(L)- File #2 MAIN_PRGRM - 698
 -(U)- File #2 MAIN_PRGRM - 700
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

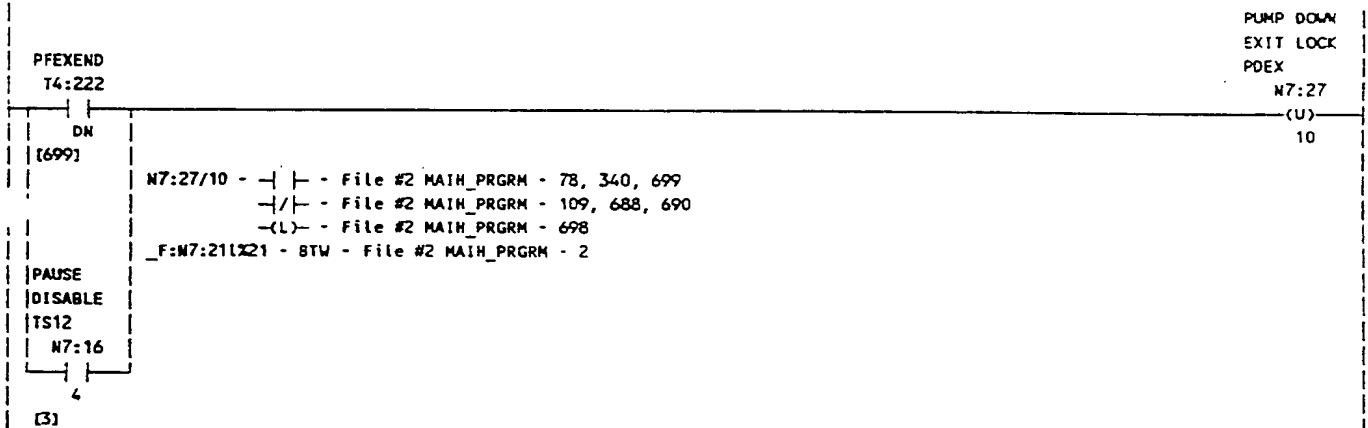
Rung #699



T4:222.DN - | | - File #2 MAIN_PRGRM - 700
 T4:222.TT - | | - File #2 MAIN_PRGRM - 98

PUMPDOWN
 EXITLOCK
 COMPLETE
 PFEXEND
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:222
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

Rung #700



N7:27/10 - | | - File #2 MAIN_PRGRM - 78,340,699
 -|/| - File #2 MAIN_PRGRM - 109,688,690
 -(L)- File #2 MAIN_PRGRM - 698
 F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

453

Rung #701

MANUAL
CONTROL
CHAMBER
VENT 1
CLOSE
M-CV1-0
N7:4

MANUAL
CHAMBER
VENT 1
CLOSE
MCVNT1CL
N7:25

0	(L)	0
(3)		
N7:25/0 - (U) - File #2 MAIN_PRGRM - 706		MANUAL
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2		CHAMBER
N7:27/11 - (L) - File #2 MAIN_PRGRM - 706		VENT 1
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2		OPEN
		MCVNT1OP
		N7:27
		(U)
		11

Rung #702

MANUAL
CONTROL
CHAMBER
VENT VALVE
CLOSE
M-CV2-0
N7:4

MANUAL
CHAMBER
VENT 2
CLOSE
MCVNT2CL
N7:25

1	(L)	1
(3)		
N7:25/1 - (U) - File #2 MAIN_PRGRM - 707		MANUAL
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2		CHAMBER
N7:27/12 - (L) - File #2 MAIN_PRGRM - 707		VENT 2
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2		OPEN
		MCVNT2OP
		N7:27
		(U)
		12

Rung #703

MANUAL
CONTROL
CHAMBER
VENT VALVE
CLOSE
M-CV3-0
N7:4

MANUAL
CHAMBER
VENT 3
CLOSE
MCVNT3CL
N7:25

2	(L)	2
(3)		
N7:25/2 - (U) - File #2 MAIN_PRGRM - 708		MANUAL
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2		CHAMBER
N7:27/13 - (L) - File #2 MAIN_PRGRM - 708		VENT 3
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2		OPEN
		MCVNT3OP
		N7:27
		(U)
		13

454

Rung #704

MANUAL
CONTROL
CHAMBER
VENT VALVE
4 CLOSE
M-CV4-0
N7:4

MANUAL
CHAMBER
VENT 4
CLOSE
MCVNT4CL
N7:25

(L)
3

(L)
3

[3]

N7:25/3 - -(U)- - File #2 MAIN_PRGRM - 709
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/14 - -(L)- - File #2 MAIN_PRGRM - 709
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CHAMBER
VENT 4
OPEN
MCVNT4OP
N7:27
(U)
14

Rung #705

MANUAL
CONTROL
CHAMBER
VENT VALVE
5 CLOSE
M-CV5-0
N7:4

MANUAL
CHAMBER
VENT 5
CLOSE
MCVNT5CL
N7:25

(L)
4

(L)
4

[3]

N7:25/4 - -(U)- - File #2 MAIN_PRGRM - 710
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:27/15 - -(L)- - File #2 MAIN_PRGRM - 710
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CHAMBER
VENT 5
OPEN
MCVNT5OP
N7:27
(U)
15

Rung #706

MANUAL
CONTROL
CHAMBER
VENT 1
OPEN
M-CV1-1
N7:6

MANUAL
CHAMBER
VENT 1
OPEN
MCVNT1OP
N7:27

(L)
11

(L)
11

[3]

N7:27/11 - -(U)- - File #2 MAIN_PRGRM - 701
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2
N7:25/0 - -(L)- - File #2 MAIN_PRGRM - 701
_F:N7:21IX21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CHAMBER
VENT 1
CLOSE
MCVNT1CL
N7:25
(U)
0

455

Rung #707

MANUAL
CONTROL
CHAMBER
VENT 2
OPEN
M-CV2-1
N7:6

MANUAL
CHAMBER
VENT 2
OPEN
MCVNT2OP
N7:27

12
[3]

(L)
12
MANUAL
CHAMBER
VENT 2
CLOSE
MCVNT2CL
N7:25
(U)
1

N7:27/12 - (U) - File #2 MAIN_PRGRM - 702
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:25/1 - (L) - File #2 MAIN_PRGRM - 702
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #708

MANUAL
CONTROL
CHAMBER
VENT 3
OPEN
M-CV3-1
N7:6

MANUAL
CHAMBER
VENT 3
OPEN
MCVNT3OP
N7:27

13
[3]

(L)
13
MANUAL
CHAMBER
VENT 3
CLOSE
MCVNT3CL
N7:25
(U)
2

N7:27/13 - (U) - File #2 MAIN_PRGRM - 703
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:25/2 - (L) - File #2 MAIN_PRGRM - 703
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

Rung #709

MANUAL
CONTROL
CHAMBER
VENT 4
OPEN
M-CV4-1
N7:6

MANUAL
CHAMBER
VENT 4
OPEN
MCVNT4OP
N7:27

14
[3]

(L)
14
MANUAL
CHAMBER
VENT 4
CLOSE
MCVNT4CL
N7:25
(U)
3

N7:27/14 - (U) - File #2 MAIN_PRGRM - 704
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:25/3 - (L) - File #2 MAIN_PRGRM - 704
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

456

Rung #710

MANUAL CONTROL
CHAMBER VENT 5
OPEN
M-CV5-1

N7:6

15

[3]

N7:27/15 - (U) - File #2 MAIN_PRGRM - 705
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:25/4 - (L) - File #2 MAIN_PRGRM - 705
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL
CHAMBER
VENT 5
OPEN
M-CVNT5OP
N7:27

(L)

15

MANUAL
CHAMBER
VENT 5
CLOSE
M-CVNT5CL
N7:25

(U)

4

Rung #711

AUTOPULSE
T4:282

TT

[158]

WATER TEST
LOCK
H2O_TST_LCK
B3

33

B3/281 - | | - File #2 MAIN_PRGRM - 712
-(U) - File #2 MAIN_PRGRM - 713

AUTOFFPULSE
T4:283

DN

[155]

WATER FLOW
SWITCH TEST
WFS_TST
B3
(L)
281

Rung #712

WATER FLOW
SWITCH TEST
WFS_TST
B3

281

[711]

WATER FLOW
SWITCH TIMER
WFS_TMR

TON
TIMER ON DELAY (EN)
TIMER: T4:330
BASE (SEC): 1.0 (DN)
PRESET: 20
ACCUM: 0

T4:330 - TON - File #2 MAIN_PRGRM - 712
LEQ - File #2 MAIN_PRGRM - 719
T4:330.ACC - LEQ - File #2 MAIN_PRGRM - 717,718,720
GEQ - File #2 MAIN_PRGRM - 717,718,719,720
T4:330.DN - | | - File #2 MAIN_PRGRM - 713
ng #713

WFS_TMR
T4:330

DN

[712]

B3/281 - | | - File #2 MAIN_PRGRM - 712
-(L) - File #2 MAIN_PRGRM - 711
-(U) - File #2 MAIN_PRGRM - 713

WATER FLOW
SWITCH TEST
WFS_TST
B3
(U)
281

457

Rung #714

CATHODE	CATHODE	CATHODE	CATHODE	WATER FLOW	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE
WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	SWITCH 5	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW
SWITCH 1	SWITCH 1	SWITCH 1	SWITCH 4	SWITCH 5	SWITCH 6	SWITCH 7	SWITCH 8	SWITCH 9	SWITCH 10
CHR1A	CHR1A	CHR1A	CHR4A	CHR18	CHR28	CHR38	CHR48	WFS9	WFS10
I:026	I:026	I:026	I:026	I:026	I:026	I:026	I:026	I:042	I:042
/	/	/	/	/	/	/	/	/	/
10	10	10	13	14	15	16	17	10	11

CATHODE	CATHODE	FLOW SWITCH
WATER FLOW	WATER FLOW	GROUP 1 OK
SWITCH 11	SWITCH 12	FTST1_OK
WFS11	WFS12	FTST1_OK
I:042	I:042	83
/	/	()
12	13	283

83/283 - | | - File #2 MAIN_PRGRM - 717

- () - File #2 MAIN_PRGRM - 714

Rung #715

CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE
WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW	WATER FLOW
SWITCH 13	SWITCH 14	SWITCH 15	SWITCH 16	SWITCH 17	SWITCH 18	SWITCH 19	SWITCH 20	SWITCH 21	SWITCH 22
WFS13	WFS14	WFS15	WFS16	WFS17	WFS18	WFS19	WFS20	WFS21	WFS22
I:042	I:042	I:042	I:042	I:056	I:056	I:056	I:056	I:056	I:056
/	/	/	/	/	/	/	/	/	/
14	15	16	17	10	11	12	13	14	15

CATHODE	CATHODE	FLOW TEST
WATER FLOW	WATER FLOW	GROUP 2 OK
SWITCH 23	SWITCH 24	FTST2_OK
WFS23	WFS24	FTST2_OK
I:056	I:056	83
/	/	()
16	17	284

83/284 - | | - File #2 MAIN_PRGRM - 717

- () - File #2 MAIN_PRGRM - 715

Rung #716

CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	CATHODE	HEATER	HEATER	HEATER	HEATER	HEATER
SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O	SHIELD H2O
FLOW	FLOW	FLOW	FLOW	H2O FLOW	H2O FLOW	FLOW	FLOW	FLOW	FLOW	FLOW
SWITCH 1	SWITCH 2	SWITCH 9	SWITCH 10	SWITCH 17	SWITCH 18	SWITCH 1	SWITCH 2	SWITCH 3	SWITCH 4	SWITCH 5
CSFS1	CSFS2	CSFS9	CSFS10	CSFS17	CSFS18	HSFS1	HSFS2	HSFS3	HSFS4	HSFS5
I:025	I:025	I:041	I:041	I:055	I:055	I:006	I:006	I:006	I:006	I:023
/	/	/	/	/	/	/	/	/	/	/
04	05	04	05	04	05	10	11	12	13	16

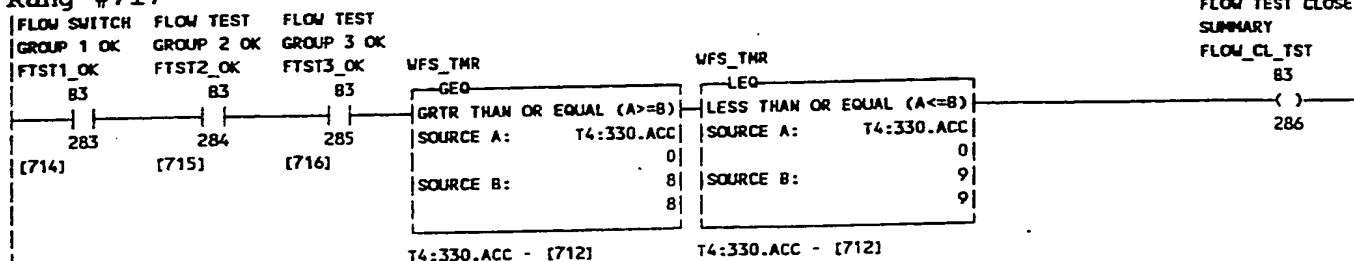
HEATER	FLOW TEST
SHIELD H2O	GROUP 3 OK
SWITCH 6	FTST3_OK
HSFS6	FTST3_OK
I:023	83
/	()
17	285

83/285 - | | - File #2 MAIN_PRGRM - 717

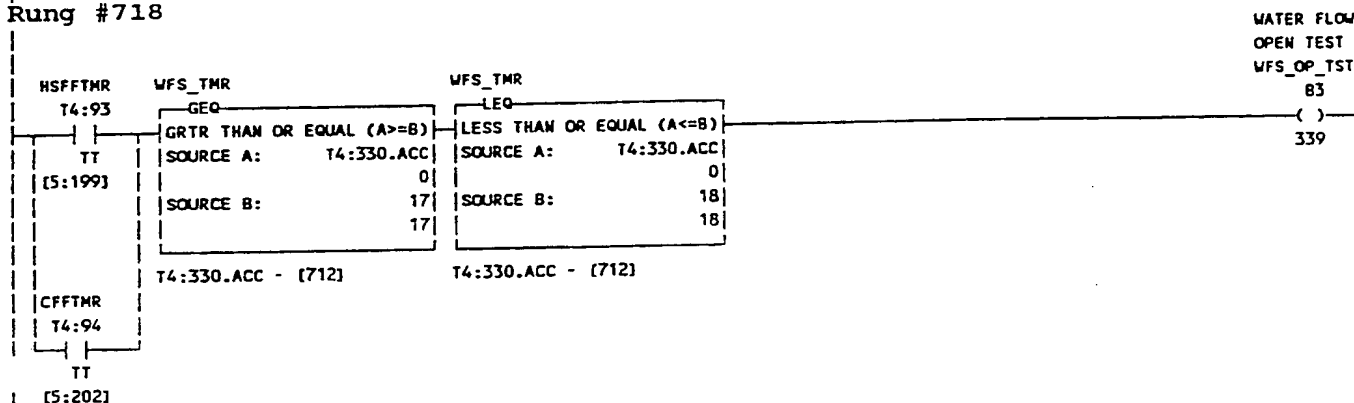
- () - File #2 MAIN_PRGRM - 716

458

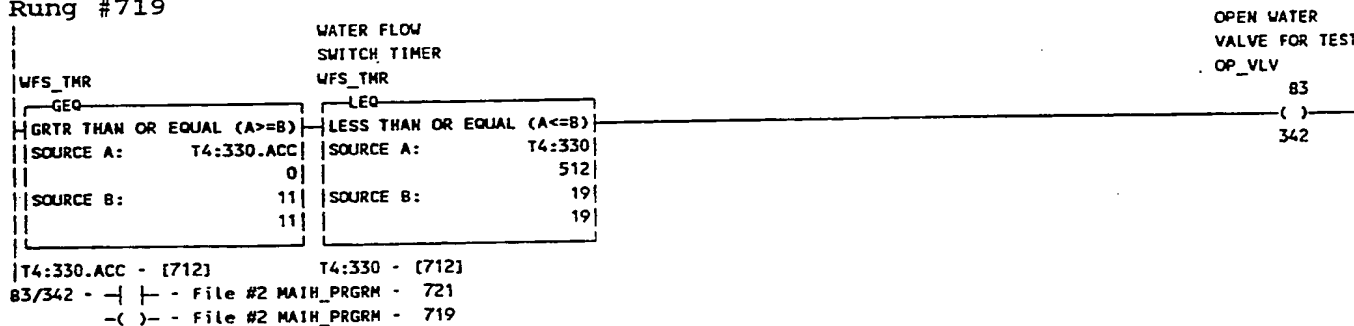
Rung #717



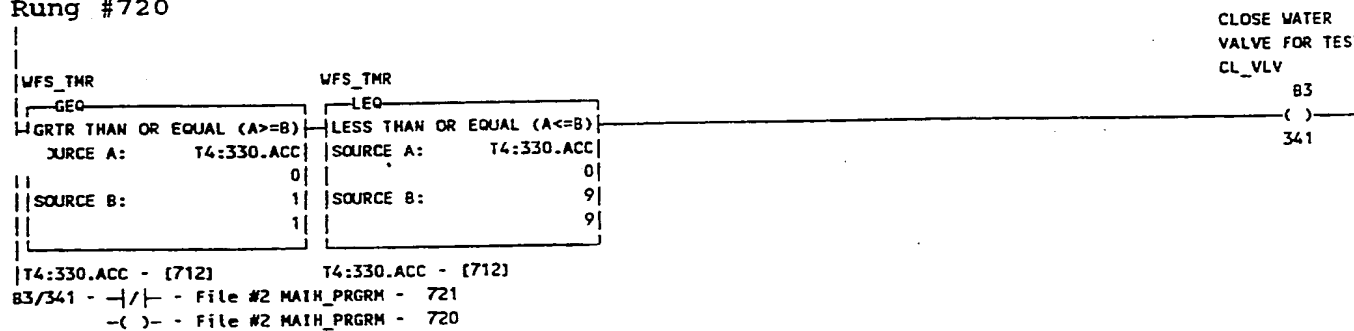
Rung #718



Rung #719

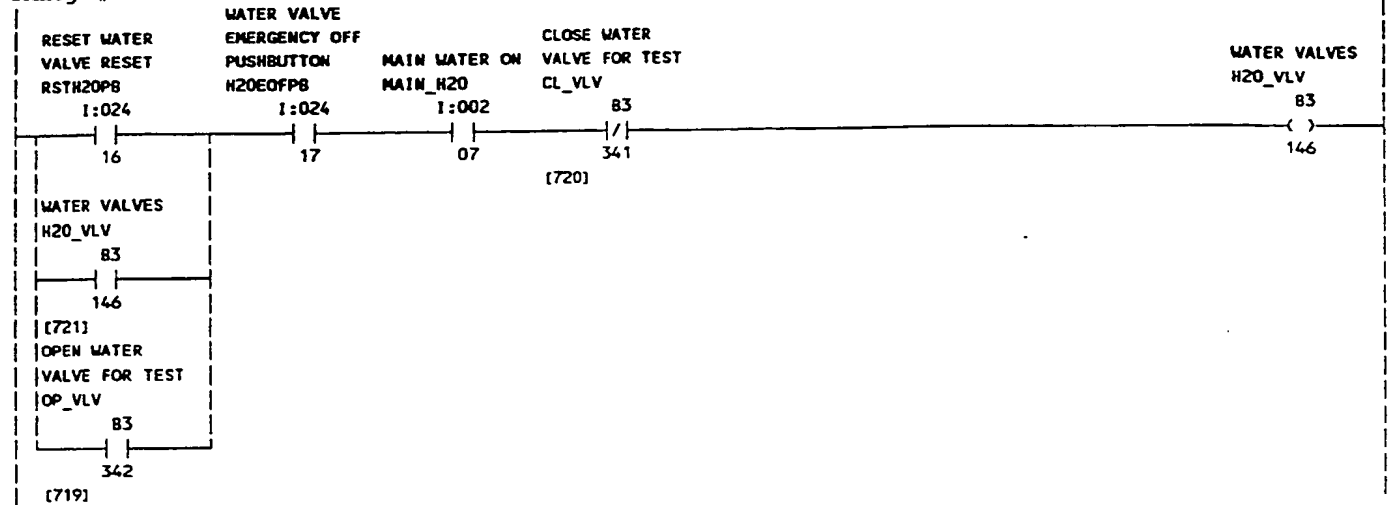


Rung #720



459

Rung #721



B3/146 - | | - File #2 MAIN_PRGRM - 721,723,728,731,734,737
 - () - File #2 MAIN_PRGRM - 721

Rung #722

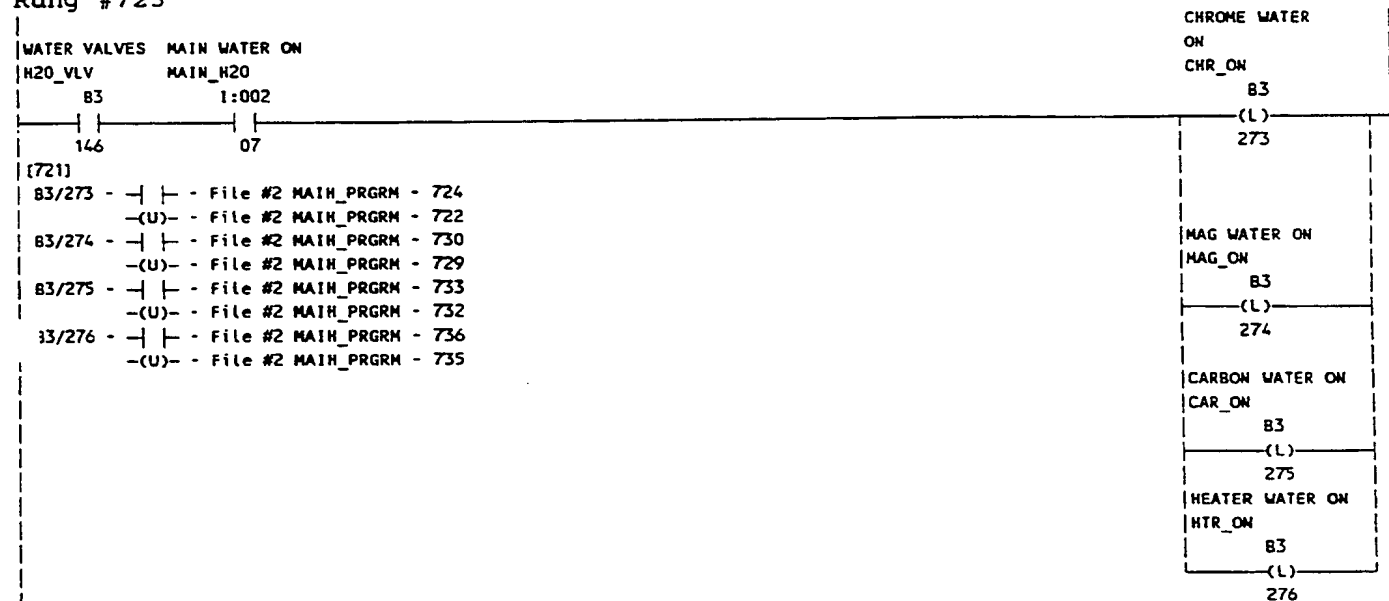


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B3/273 - | | - File #2 MAIN_PRGRM - 724
          -(L)- - File #2 MAIN_PRGRM - 723
          -(U)- - File #2 MAIN_PRGRM - 722

```

Rung #723



460

Rung #724

CHROME WATER

ON

CHR_ON

83

CHR_OF_DLY

T4:322

273

DN

[723]

[728]

0:030/16 - | - File #2 MAIH_PRGRM - 725

0:030/17 - | - File #2 MAIH_PRGRM - 725

CHROME RETURN
VALVE 3
CHRTV3

0:030

16

CHROME RETURN
VALVE 4
CHRTV4

0:030

17

Rung #725

CHROME SUPPLY

VALVE 1

CHSU1

0:030

14

CHROME SUPPLY

VALVE 2

CHSU2

0:030

15

CHROME RETURN

VALVE 3

CHRTV3

0:030

16

CHROME RETURN

VALVE 4

CHRTV4

0:030

17

CHROME WATER OK
CHR-OK

83

277

[728]

[728]

[724]

[724]

83/277 - | - File #2 MAIH_PRGRM - 235,236,238,242

-|/ - File #2 MAIH_PRGRM - 237,240,243

-() - File #2 MAIH_PRGRM - 725

Rung #726

; SUPPLY

VALVE 5

MGSUV5

0:044

14

MAG SUPPLY

VALVE 6

MGSUV6

0:044

15

MAG RETURN

VALVE 7

MGRTV7

0:044

16

MAG RETURN

VALVE 8

MGRTV8

0:044

17

MAG WATER OK
MAG_OK

83

278

[731]

[731]

[730]

[730]

83/278 - | - File #2 MAIH_PRGRM - 267,268,270,274

-|/ - File #2 MAIH_PRGRM - 269,272,275

-() - File #2 MAIH_PRGRM - 726

Rung #727

CARBON SUPPLY

VALVE 9

CASUV9

0:060

14

CARBON SUPPLY

VALVE 10

CASUV10

0:060

15

CARBON RETURN

VALVE 11

CARTV11

0:060

16

CARBON RETURN

VALVE 12

CARTV12

0:060

17

CARBON WATER OK
CAR_OK

83

279

[734]

[734]

[733]

[733]

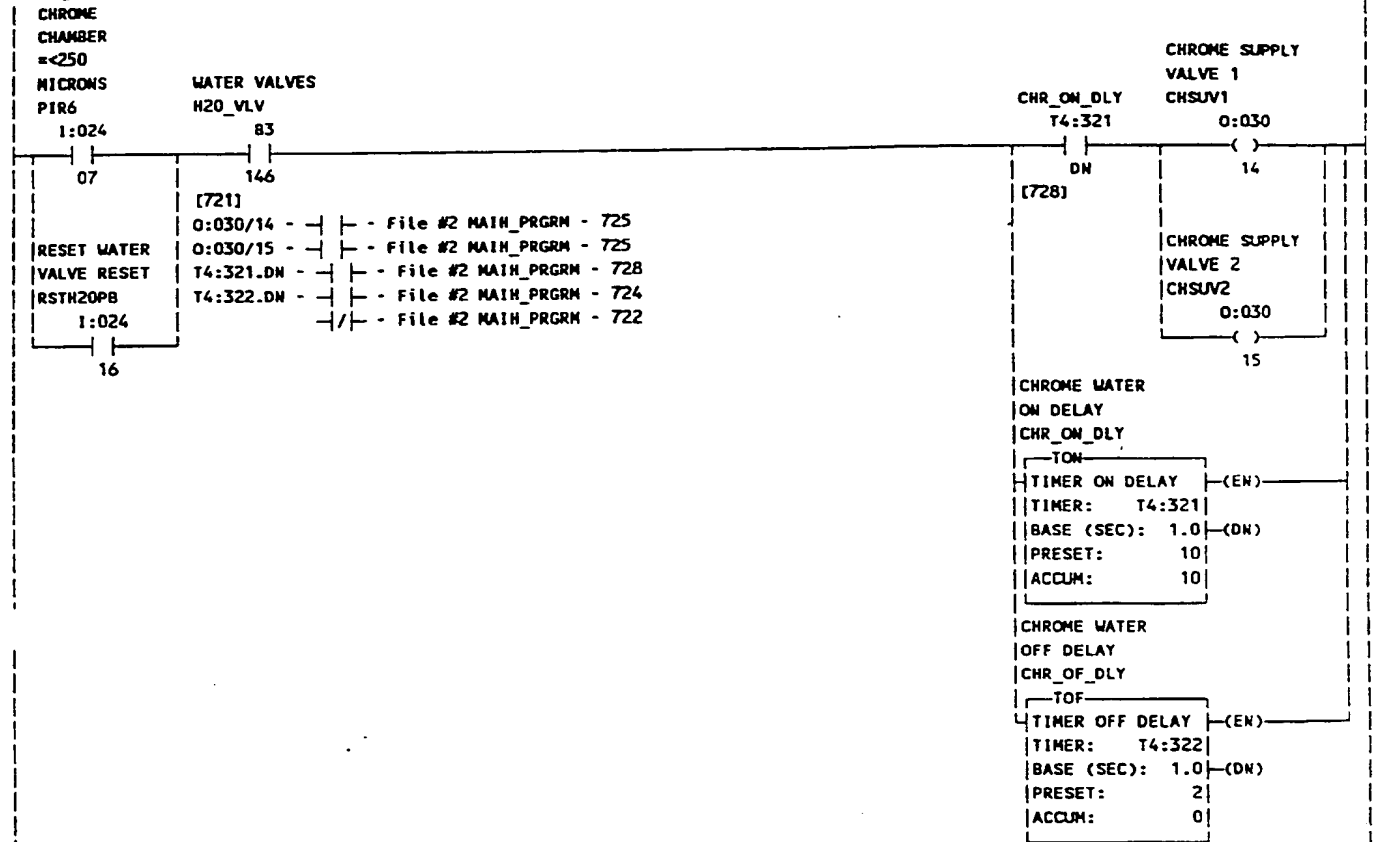
83/279 - | - File #2 MAIH_PRGRM - 299,300

-() - File #2 MAIH_PRGRM - 727

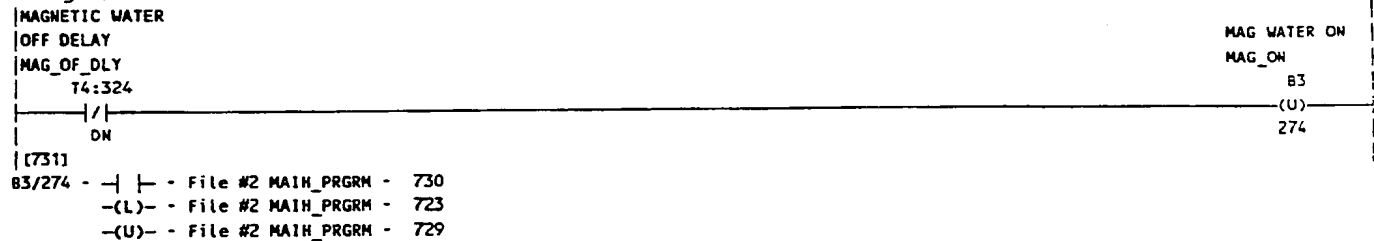
461

PCT/US 92/00722

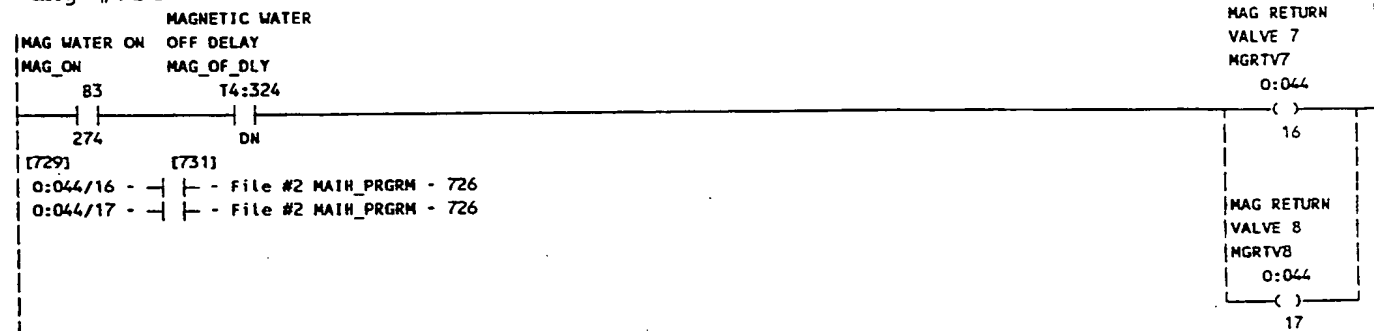
Rung #728



Rung #729

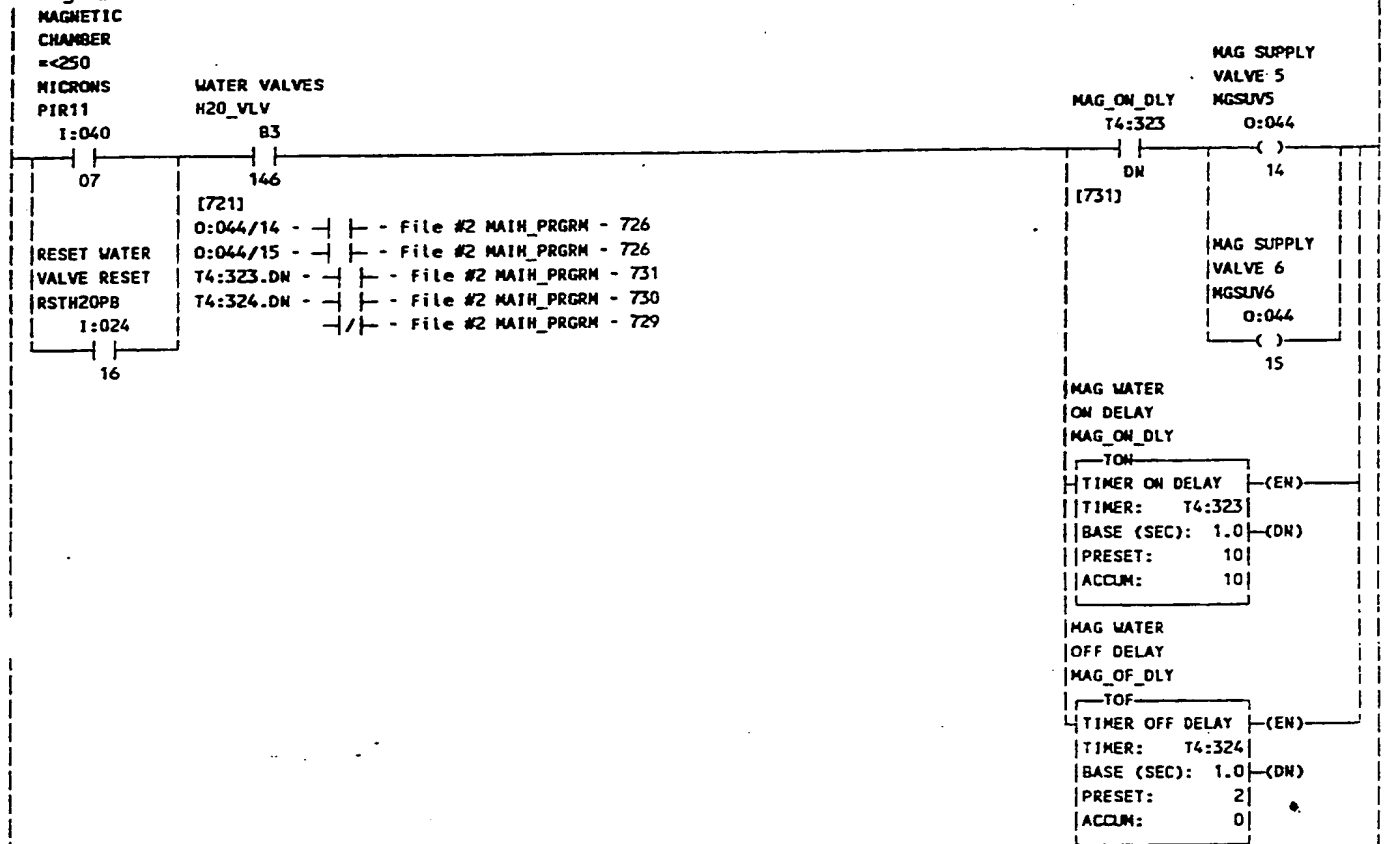


Rung #730

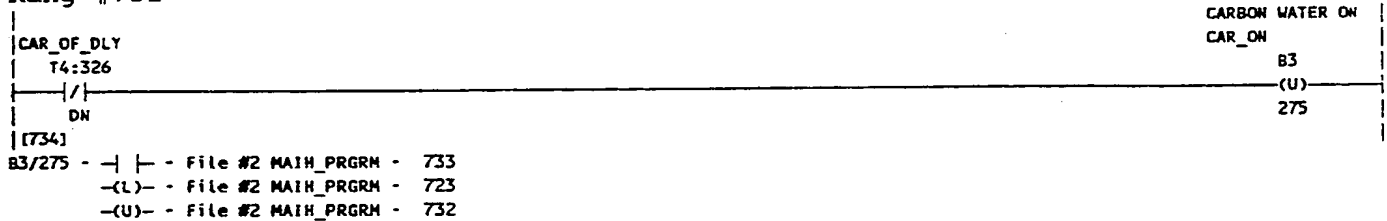


462

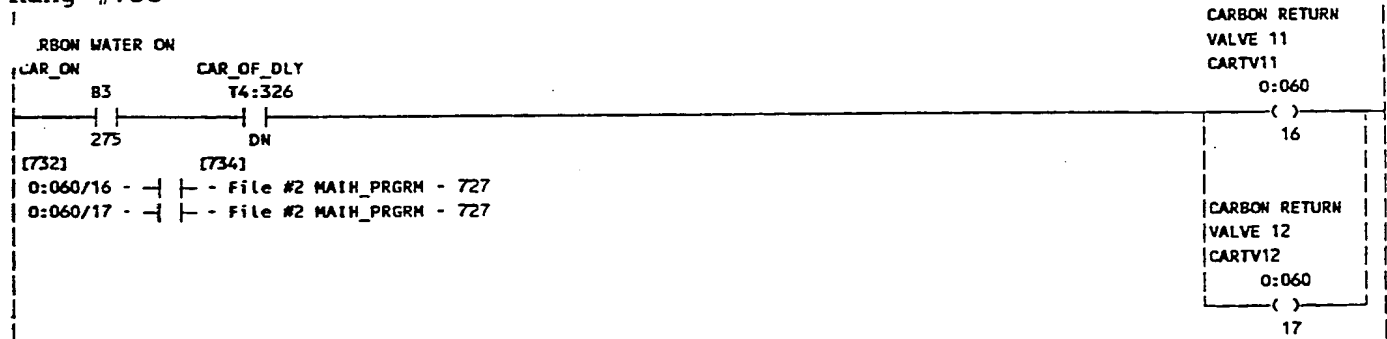
Rung #731



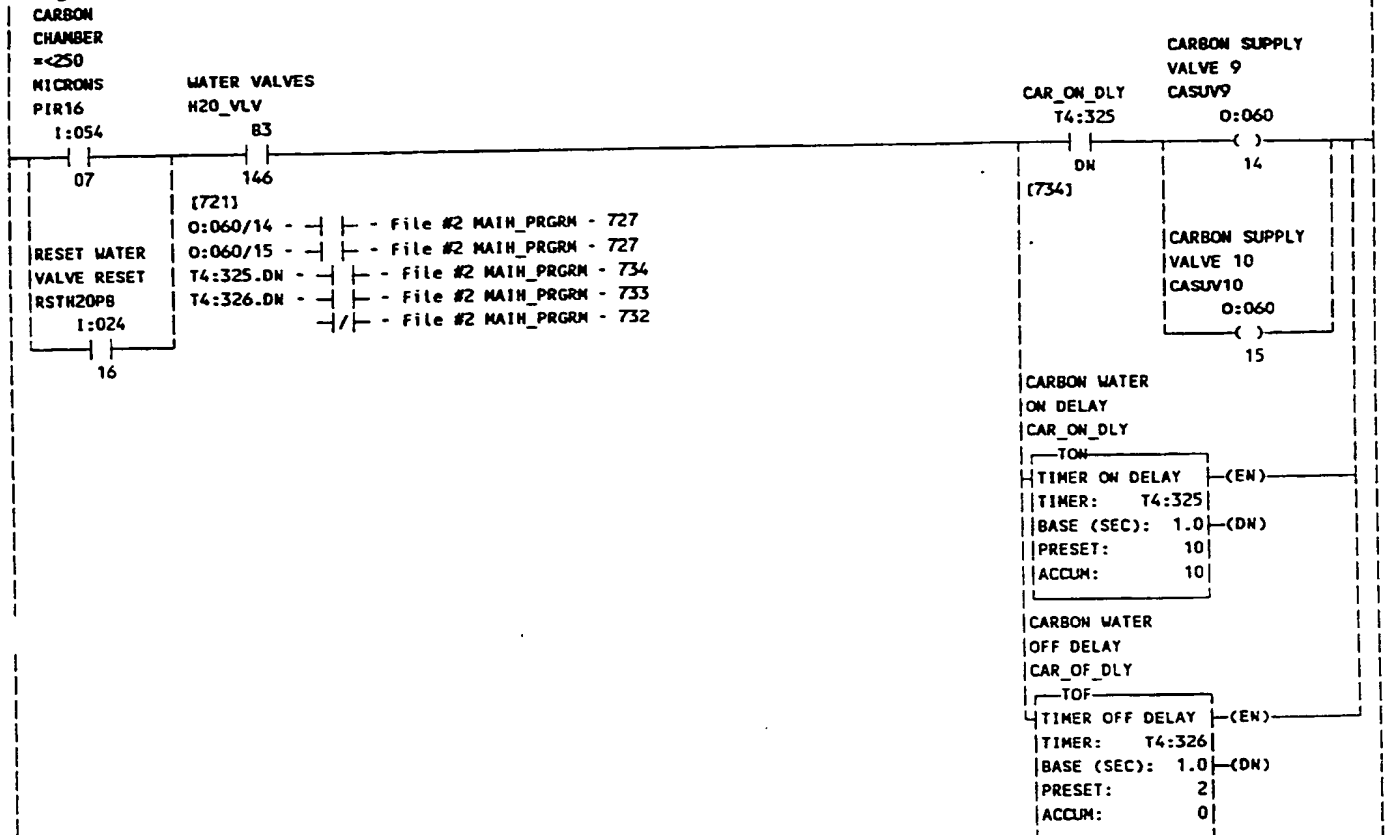
Rung #732



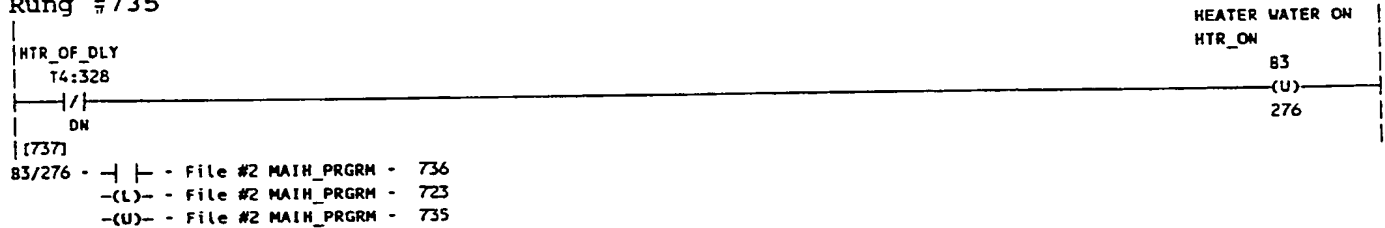
Rung #733



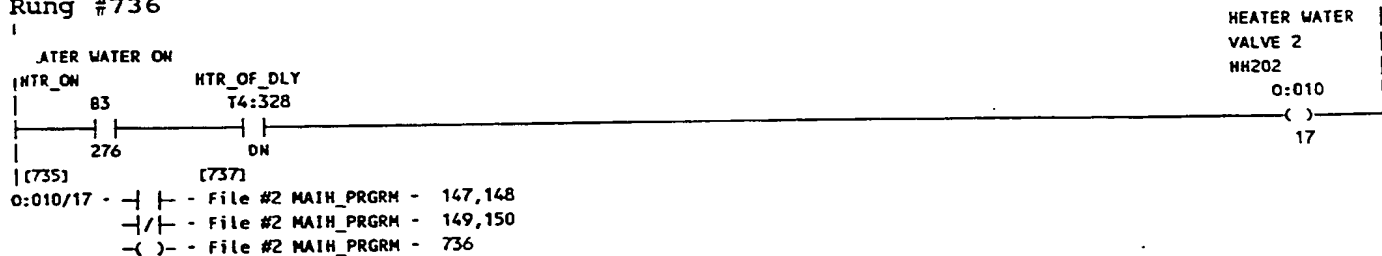
Rung #734



Rung #735



Rung #736



464

Rung #737

HEATER 1 CHROME
CHAMBER CHAMBER
=<250 =<250

MICRONS MICRONS
PIR2 PIR6

WATER VALVES
H2O_VLV

1:004

1:024

83

10

07

146

[721]

0:010/16 - | | - File #2 MAIN_PRGRM - 147, 148

- | | - File #2 MAIN_PRGRM - 149, 150

T4:327.DN - | | - File #2 MAIN_PRGRM - 737

T4:328.DN - | | - File #2 MAIN_PRGRM - 736

- | | - File #2 MAIN_PRGRM - 735

RESET WATER
VALVE RESET
RSTH20PB

1:024

16

HEATER WATER
VALVE 1

HTR_ON_DLY
T4:327

0:010

DN

16

[737]

HEATER WATER
ON DELAY
HTR_ON_DLY

TON
TIMER ON DELAY (EN)
TIMER: T4:327
BASE (SEC): 1.0 (DN)
PRESET: 10
ACCUM: 10

HEATER WATER
OFF DELAY
HTR_OF_DLY

TOF
TIMER OFF DELAY (EN)
TIMER: T4:328
BASE (SEC): 1.0 (DN)
PRESET: 2
ACCUM: 0

Rung #738

JUMP TO CRYO
REGEN
TO CRGN

JSR
JUMP TO SUBROUTINE
FILE #: U:3
INPUT PAR:
RETURN PAR:

Rung #739

JUMP TO RETURN
CONVEYOR SUBRTN
JMP_TO_RTN

JSR
JUMP TO SUBROUTINE
FILE #: U:4
INPUT PAR:
RETURN PAR:

Rung #740

GOTO FAULT
RUNGS
TO_FLT

JSR
JUMP TO SUBROUTINE
FILE #: U:5
INPUT PAR:
RETURN PAR:

465

Rung #741

JUMP TO TECH
RUNGS
JMP_TR

JSR	
JUMP TO SUBROUTINE	
FILE #:	U:6
INPUT PAR:	
RETURN PAR:	

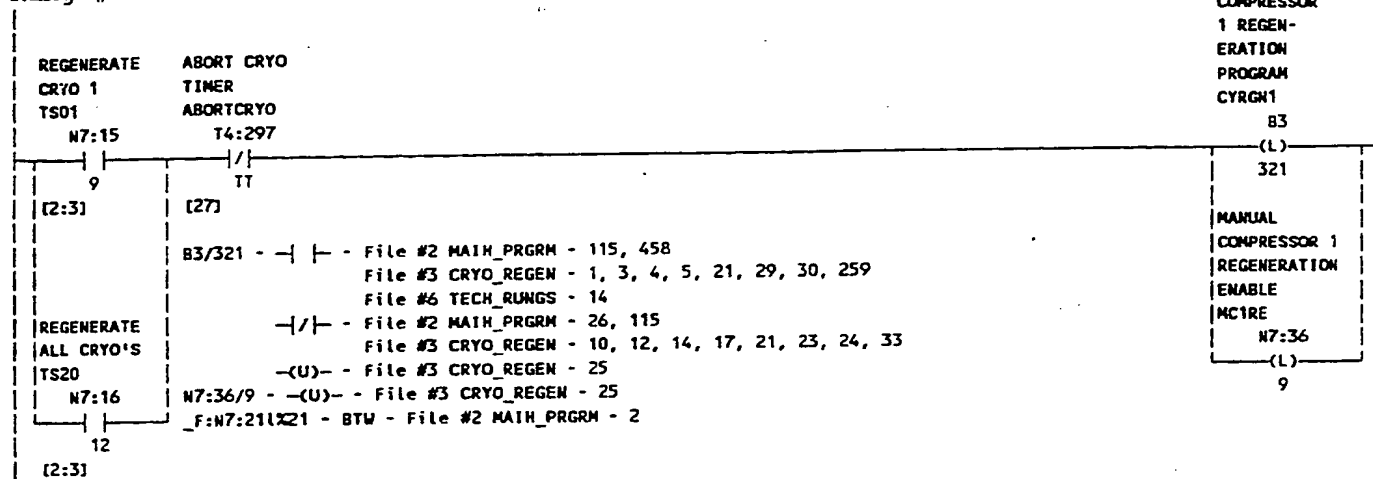
Rung #742

[END]

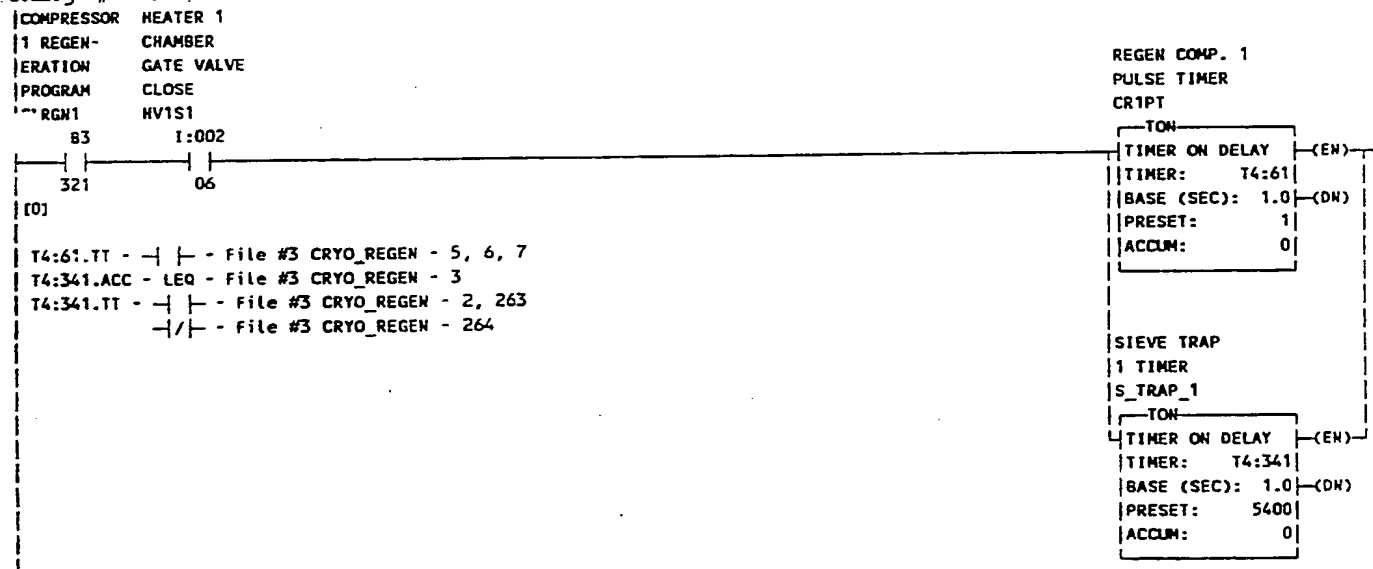
466

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Rung #000

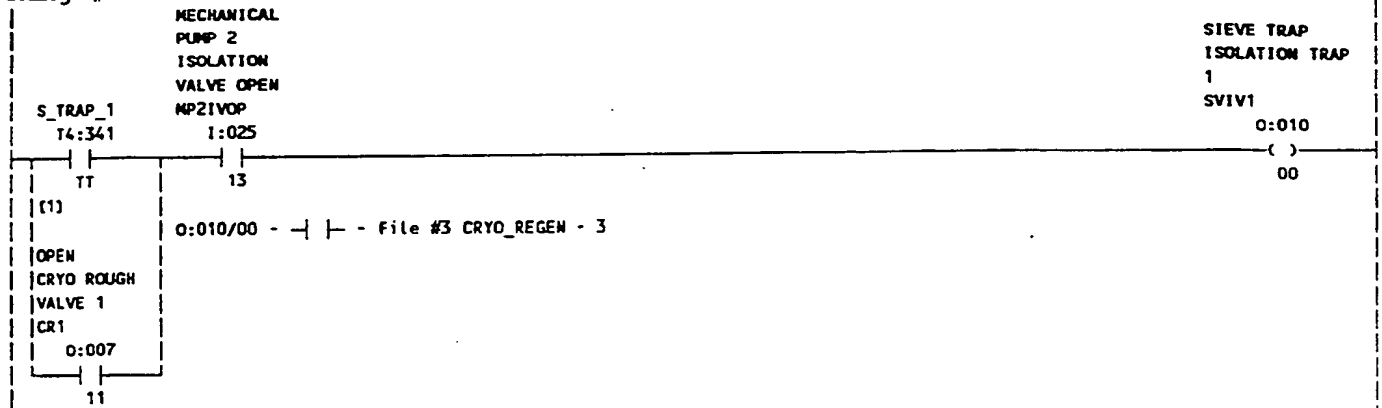


Rung #001

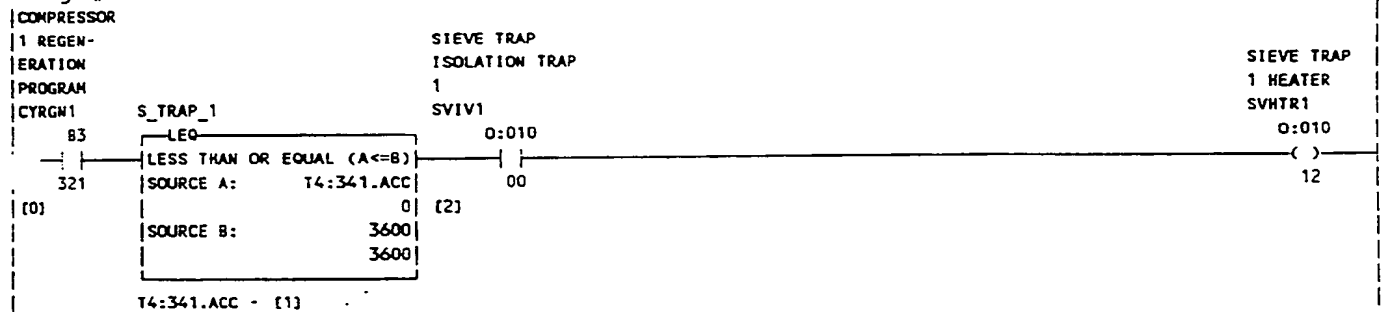


467

Rung #002



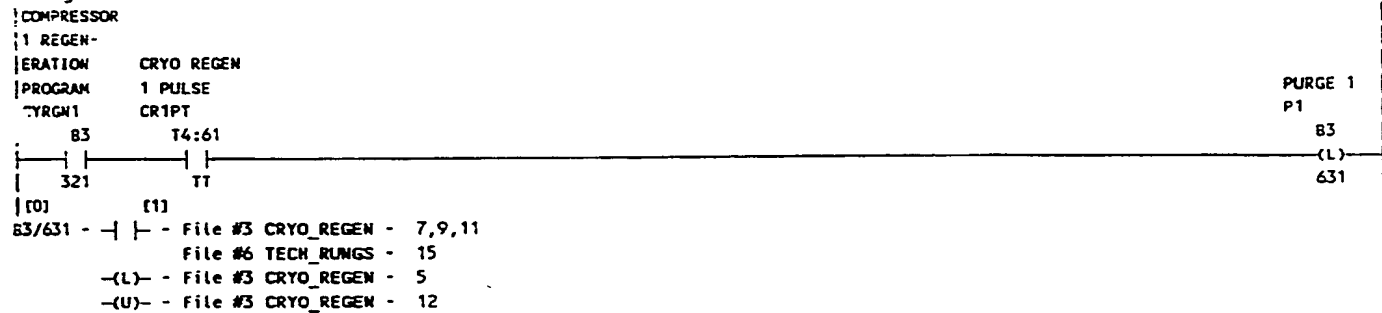
Rung #003



Rung #004



Rung #005



468

Rung #006

CRYO REGEN
1 PULSE
CR1PT

T4:61

TT

[1]

MANUAL
CONTROL
STOP CRYO
COMPRESSOR
1

M-CY1-0

N7:8

5

[2:3]

MAIN WATER ON
MAIN_W20
1:002

/

07

0:010/04 - | | - File #2 MAIN_PRGRM - 437
File #3 CRYO_REGEN - 260
File #6 TECH_RUNGS - 19
--(L)-- File #2 MAIN_PRGRM - 26
N7:29/5 - --(U)-- File #2 MAIN_PRGRM - 26
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:34/5 - --(L)-- File #2 MAIN_PRGRM - 26
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

ENABLE
CRYO
COMPRESSOR
1
CY1

0:010

(U)

04

MANUAL CRYO
COMPRESSOR 1
STOP
MTCYC1STOP
N7:29

(L)

5

MANUAL CRYO
COMPRESSOR 1
RUN
MTCYC1RUN
N7:34

(U)

5

Rung #007

CRYO REGEN
PURGE 1 1 PULSE
P1 CR1PT

B3

631

TT

OPEN
CRYO ROUGH
VALVE 1
CR1

0:007

/

11

[5]

[1]

[15]

0:007/06 - | | - File #3 CRYO_REGEN - 8
File #6 TECH_RUNGS - 16
--(L)-- File #3 CRYO_REGEN - 7
--(U)-- File #3 CRYO_REGEN - 10

OPEN PURGE
VALVE 1
MIF1

0:007

(L)

06

Rung #008

OPEN PURGE
VALVE 1
MIF1

0:007

06

[7]

0:007/03 - | | - File #3 CRYO_REGEN - 9
--(L)-- File #3 CRYO_REGEN - 8

ENABLE
PURGE
HEATER 1
MIF1

0:007

(L)

03

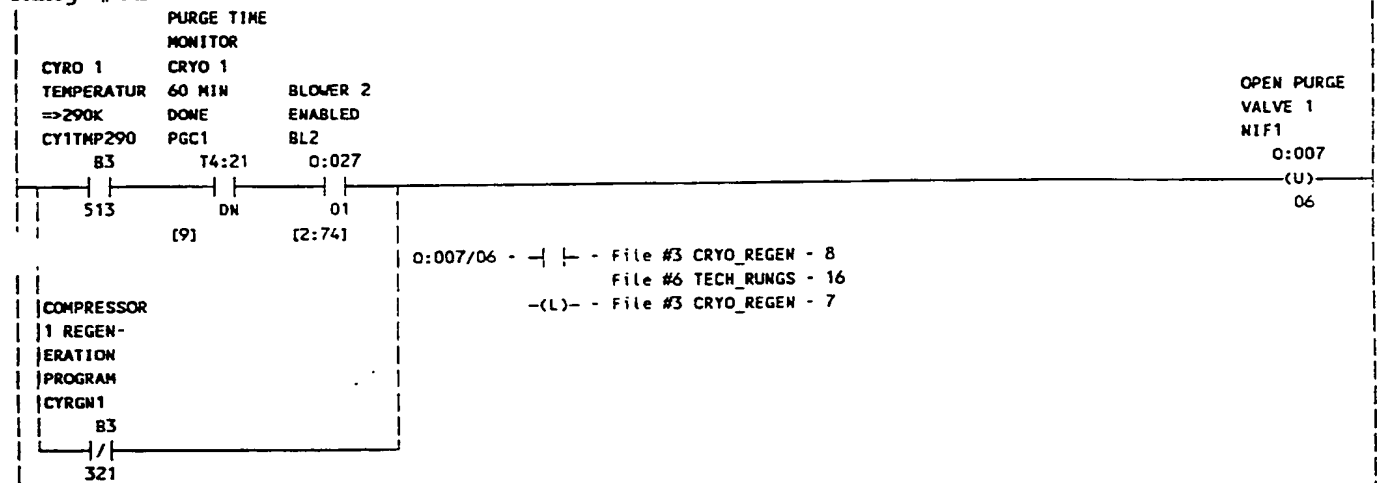
469

Rung #009

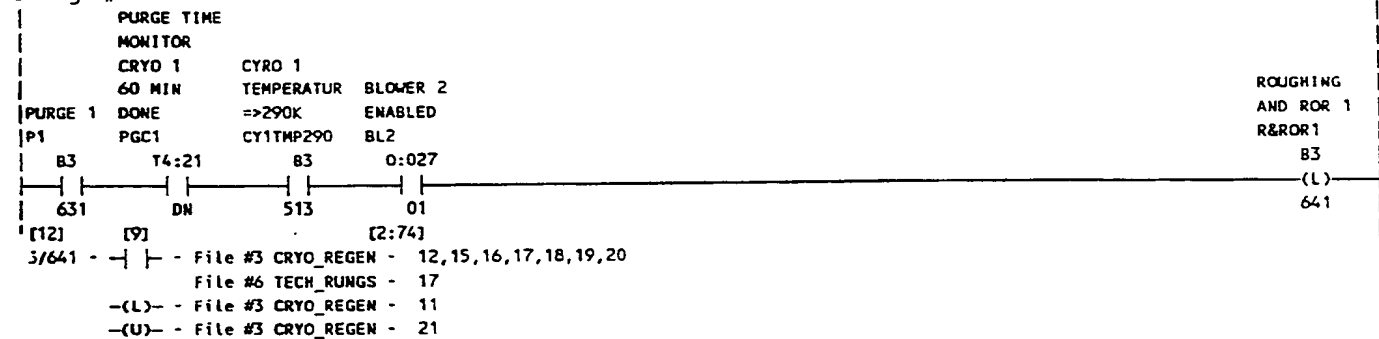


T4:21.ACC - GEQ - File #3 CRYO_REGEN - 30
 T4:21.DN - | - File #3 CRYO_REGEN - 10,11,262
 T4:21.TT - | - File #6 TECH_RUNGS - 15

Rung #010

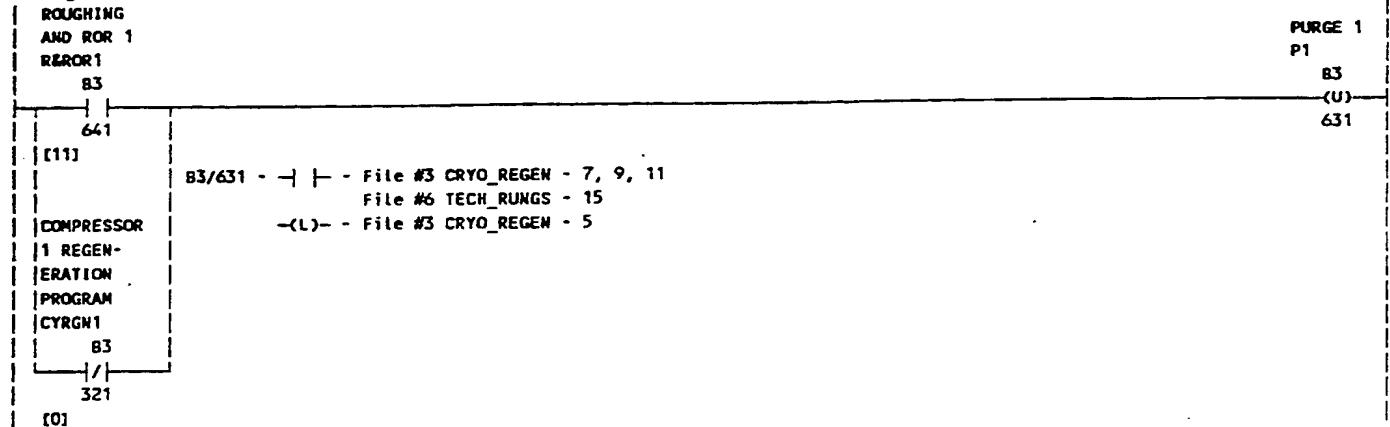


Rung #011

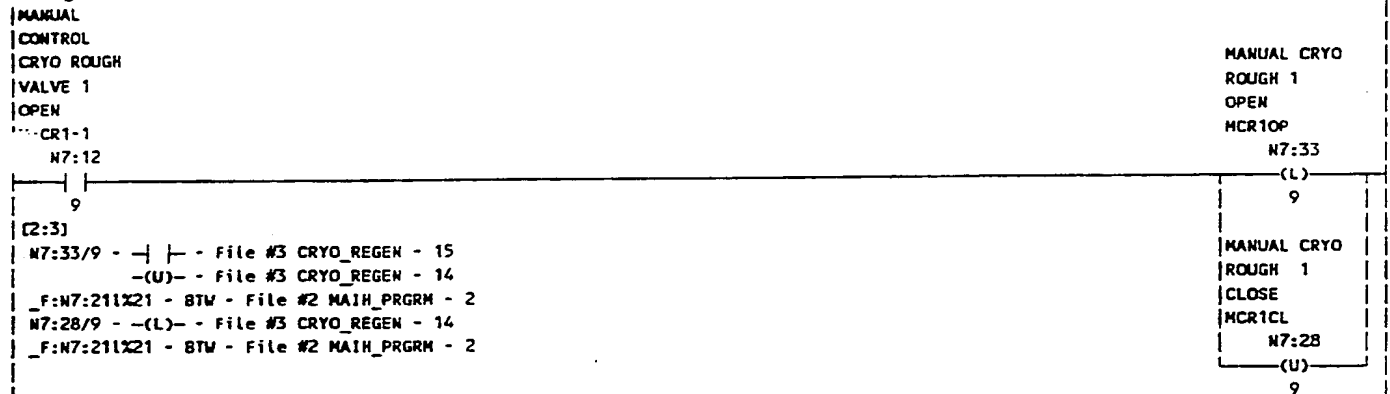


470

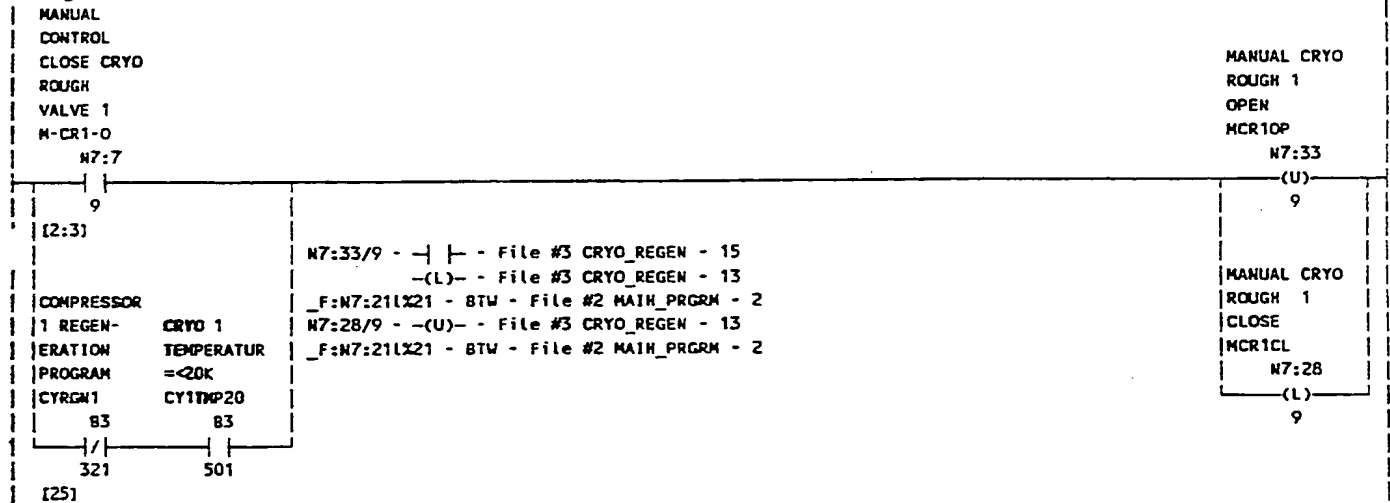
Rung #012



Rung #013

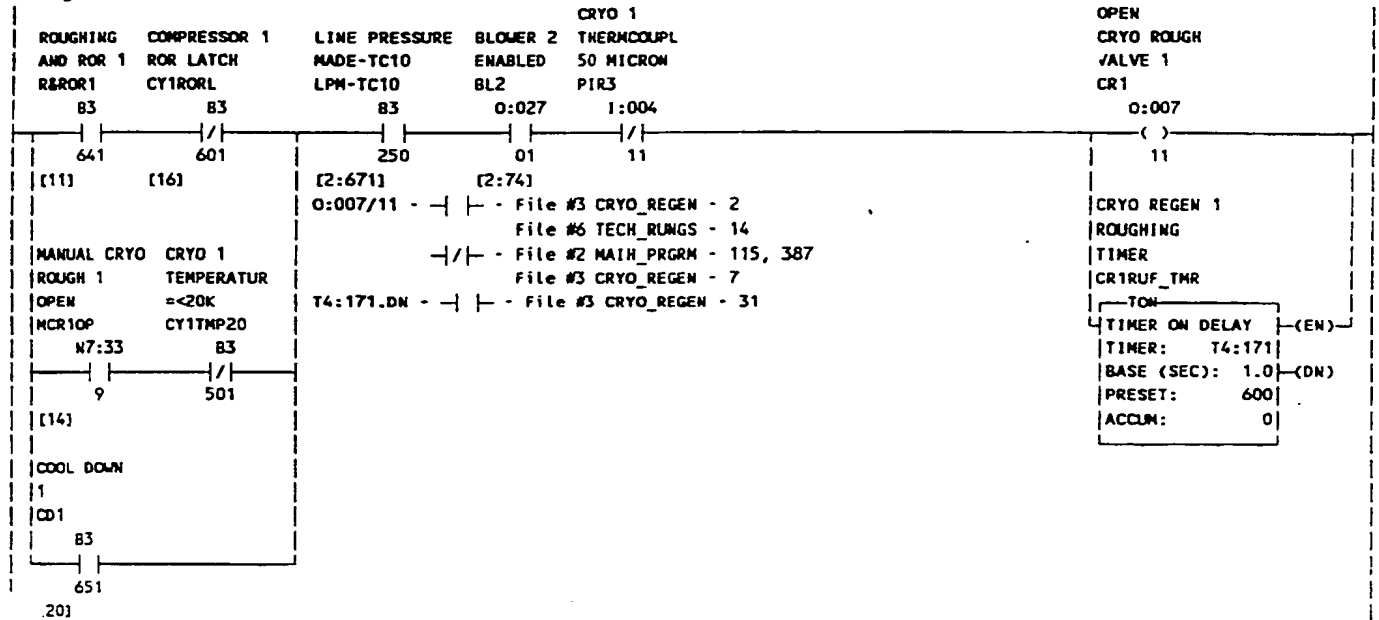


Rung #014

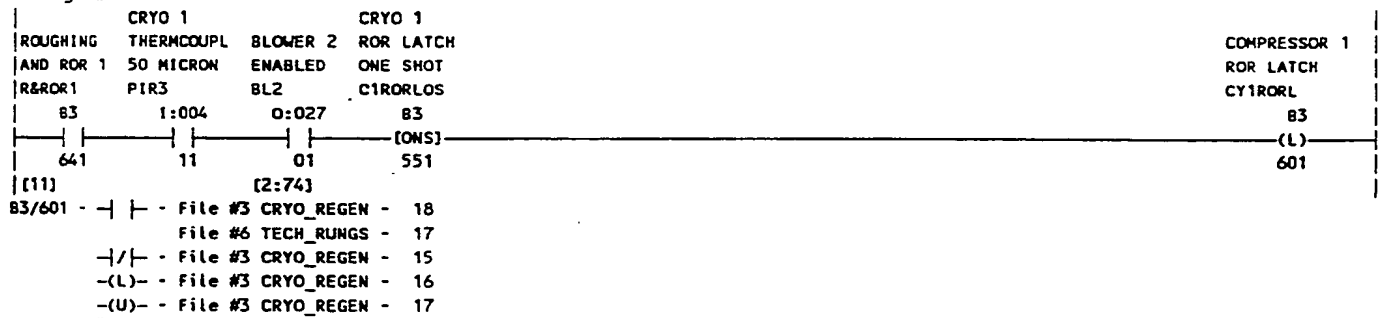


471

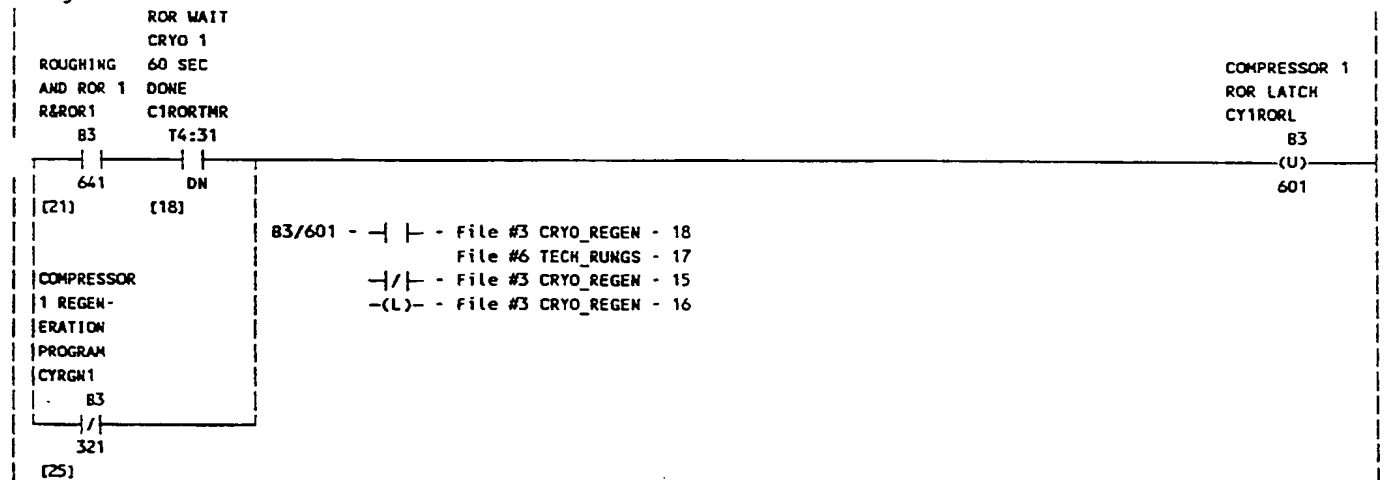
Rung #015



Rung #016



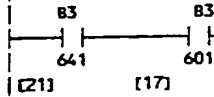
Rung #017



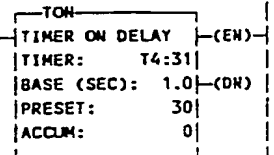
472

Rung #018

ROUGHING COMPRESSOR 1
AND ROR 1 ROR LATCH
REROR1 CY1RORL



ROR WAIT
COMPRESSOR 1
60 SEC
C1RORTMR

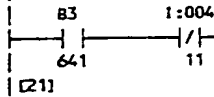


T4:31.DN - | | - File #3 CRYO_REGEN - 17,20

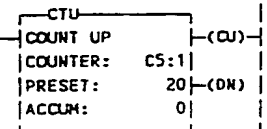
T4:31.TT - | | - File #6 TECH_RUNGS - 18

Rung #019

CRYO 1
ROUGHING THERMCOUPL
AND ROR 1 50 MICRON
REROR1 PIR3



REROUGH
COUNTER
COMPRESSOR
1
C1RERUF



.1 - CTU - File #3 CRYO_REGEN - 19

RES - File #3 CRYO_REGEN - 23

CS:1.DN - | | - File #2 MAIN_PRGRM - 623

Rung #020

CRYO 1 ROR WAIT CRYO 1 CRYO 1
ROUGHING THERMCOUPL 60 SEC TEMPERATUR
AND ROR 1 50 MICRON DONE =<20K
REROR1 PIR3 C1RORTMR CY1TMP20



63/651 - | | - File #2 MAIN_PRGRM - 26,115

File #3 CRYO_REGEN - 15,21,22,25

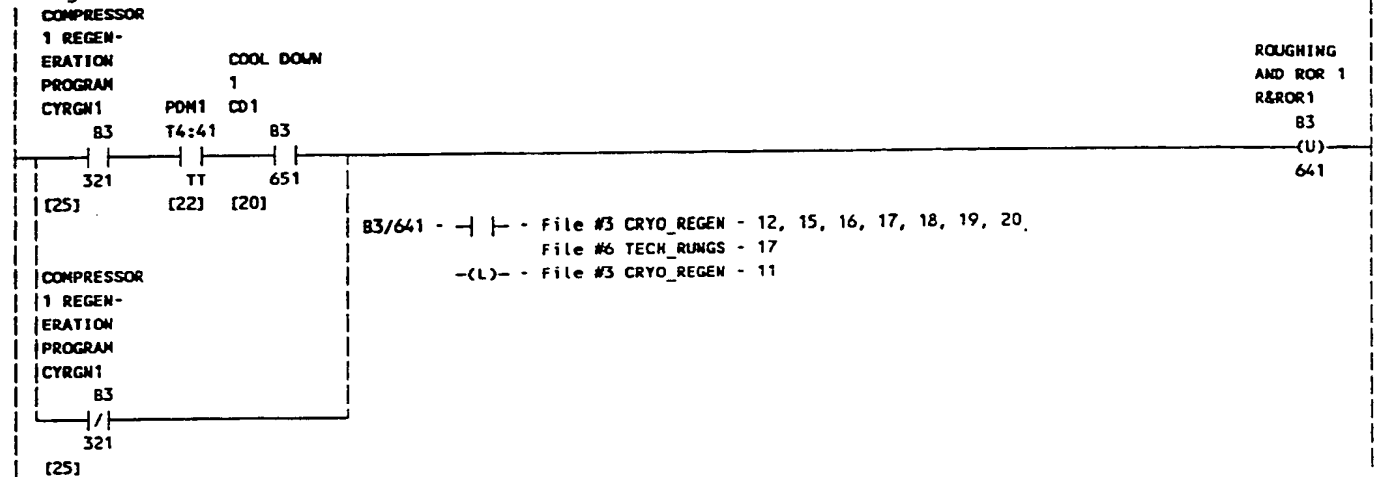
File #6 TECH_RUNGS - 19

-(L)- - File #3 CRYO_REGEN - 20

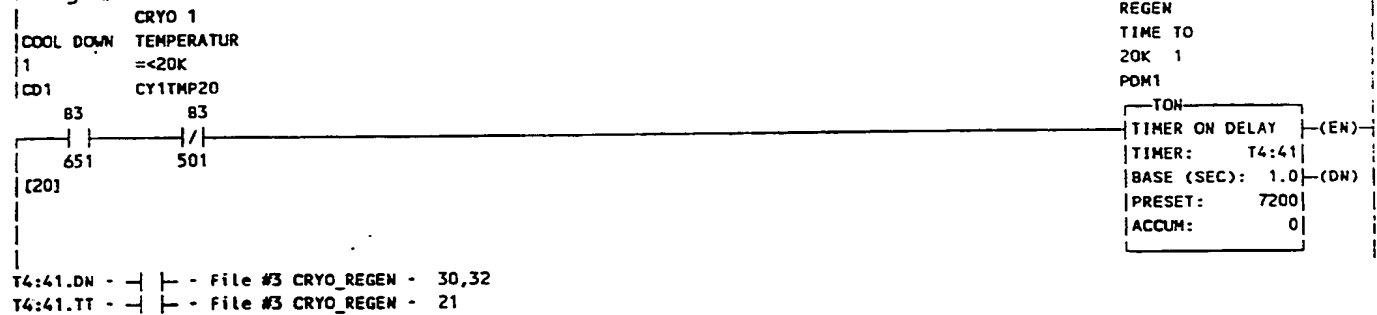
-(U)- - File #3 CRYO_REGEN - 24

473

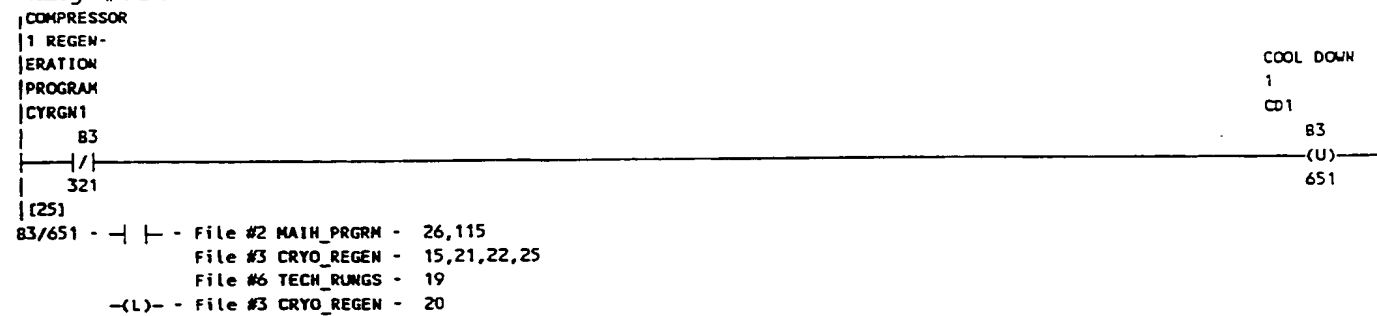
Rung #021



Rung #022



[25]
C5:1 - CTU - File #3 CRYO_REGEN - 19
RES - File #3 CRYO_REGEN - 23
C5:1.DN - | | - File #2 MAIN_PRGRM - 623
Rung #024



474

BASE : Rung #023

COMPRESSOR	CRYO 1
1 REGEN-	COUNTER
ERATION	RESET
PROGRAM	ONE SHOT
CYRGN1	C1CROS

REROUGH
COUNTER
COMPRESSOR
1
C1RERUF

B3 B3
| / | — [ONS]
321 561

CS:1 - CTU - File #3 CRYO_REGEN - 19
CS:1.DH - | | - File #2 MAIN_PRGRM - 624

PAUSE
DISABLE
TS12
N7:16

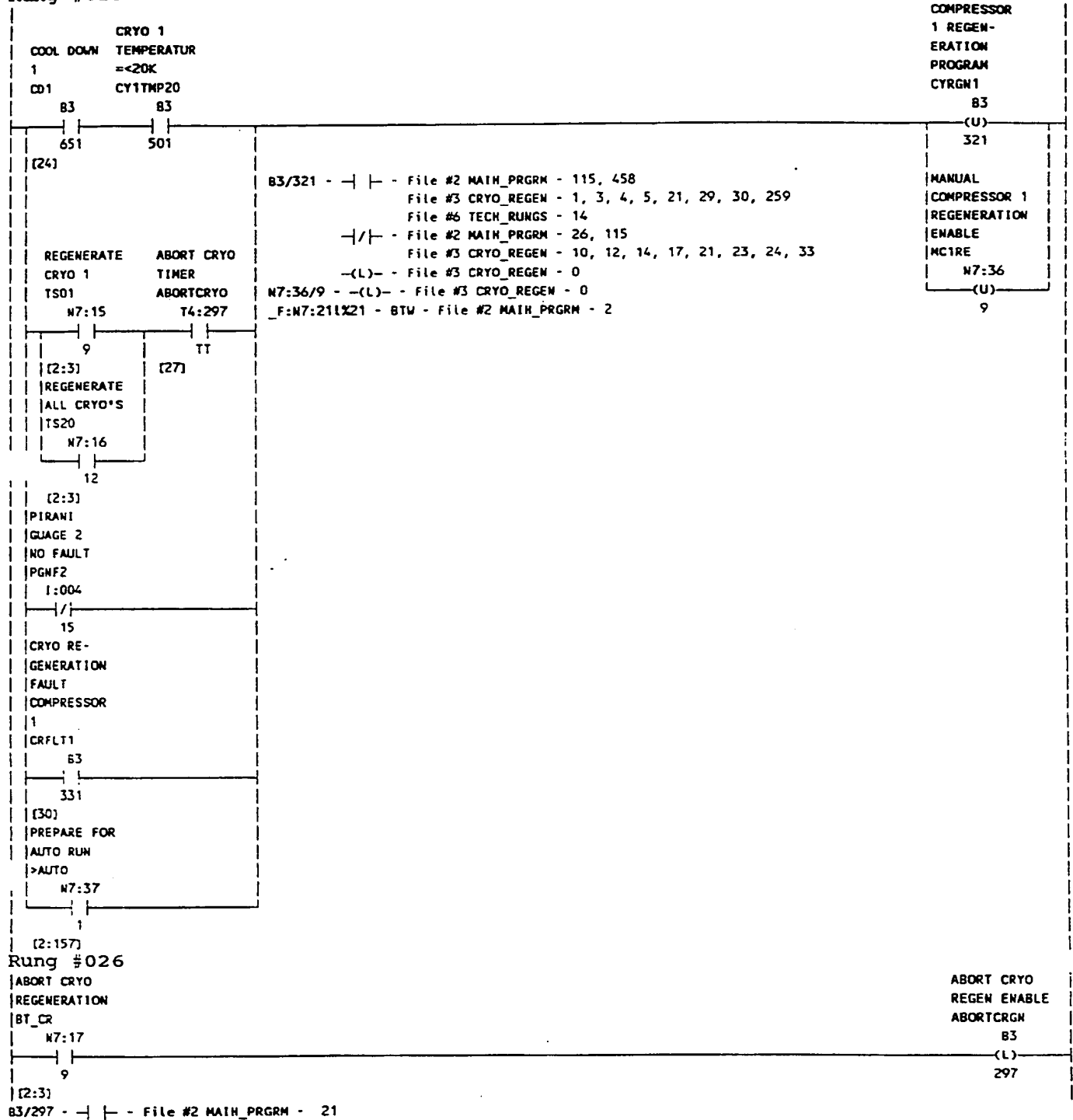
[2:3]

[RES]—

475

-(U)- - File #3 CRYO_REGEN - 24

Rung #025



476

File #3 CRYO_REGEN - 27
-(L)- - File #3 CRYO_REGEN - 26
-(U)- - File #3 CRYO_REGEN - 28

Rung #027

ABORT CRYO
REGEN ENABLE
ABORTCRGW

83
T4:297
[26]

ABORT CRYO
REGEN TIMER
ABORTCRYO

TON
TIMER ON DELAY (EN)
TIMER: T4:297
BASE (SEC): 1.0 (DN)
PRESET: 10
ACCUM: 0

T4:297.DN - | | - File #3 CRYO_REGEN - 28
T4:297.TT - | | - File #2 MATH_PRGRM - 91
File #3 CRYO_REGEN - 25,238,239,240,241,242,243,244
|/| - File #3 CRYO_REGEN - 0,34,38,42,46,52,53,57,63

Rung #028

ABORTCRYO
T4:297

DN
[27]

ABORT CRYO
REGEN ENABLE
ABORTCRGW

83
(U)
297

/297 - | | - File #2 MATH_PRGRM - 21
File #3 CRYO_REGEN - 27
-(L)- - File #3 CRYO_REGEN - 26
-(U)- - File #3 CRYO_REGEN - 28

Rung #029

COMPRESSOR HEATER 1
1 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSE
CYRGW1 HV1S1

83 I:002
321 06
[25]

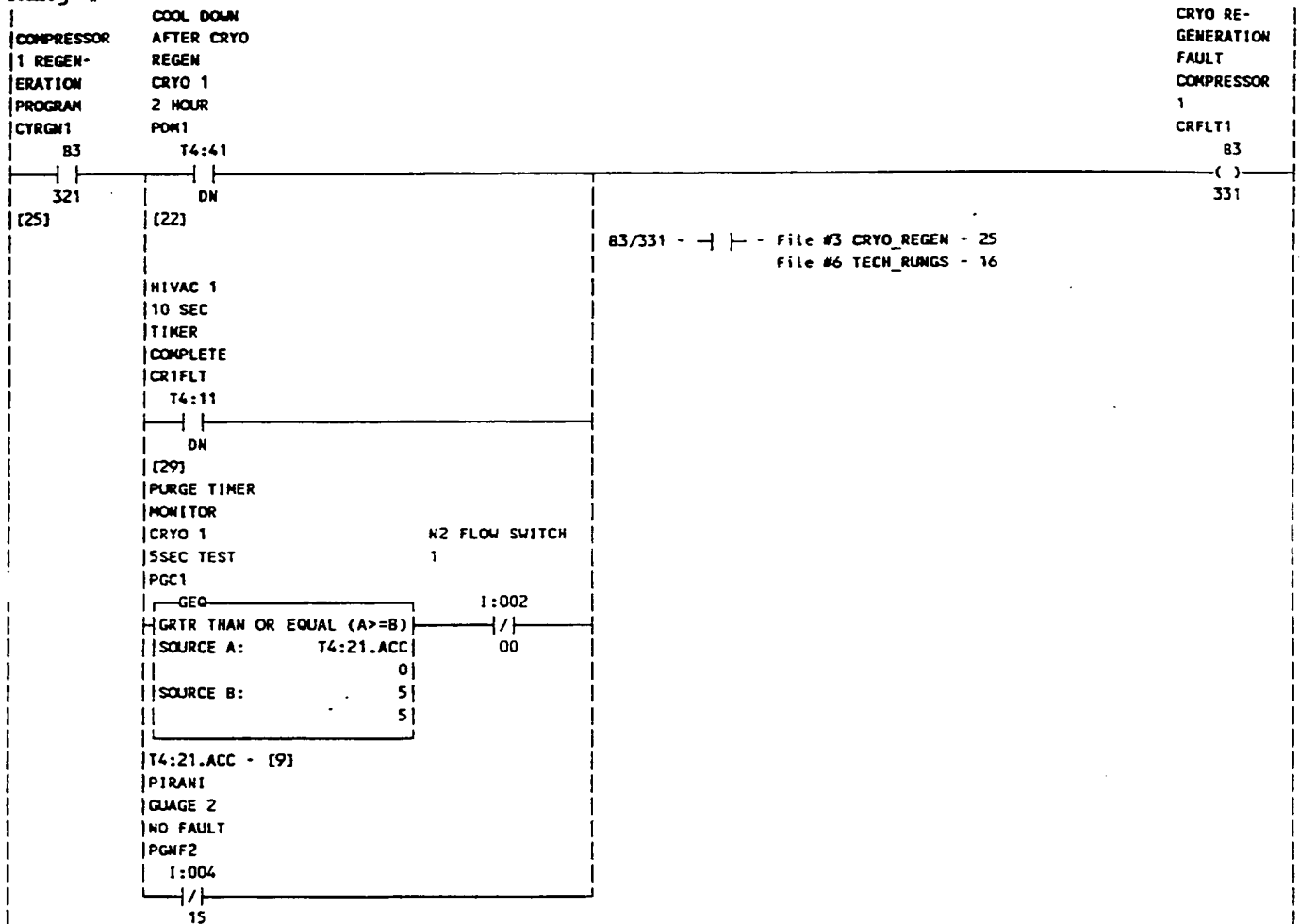
CRYO REGEN
COMPRESSOR 1
HV1 FAULT
CR1FLT

TON
TIMER ON DELAY (EN)
TIMER: T4:11
BASE (SEC): 1.0 (DN)
PRESET: 30
ACCUM: 0

T4:11.DN - | | - File #3 CRYO_REGEN - 30

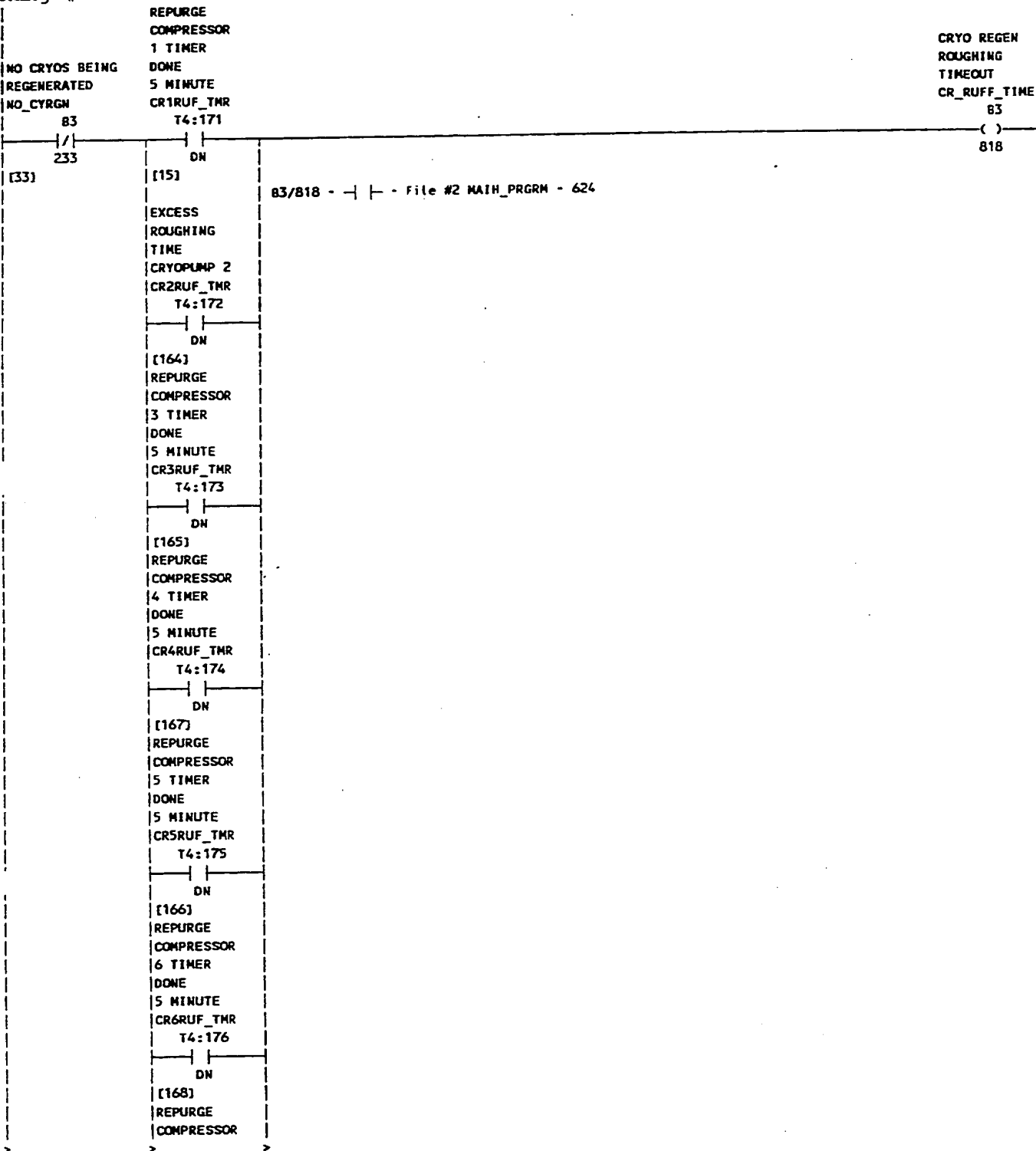
477

Rung #030



478

Rung #031

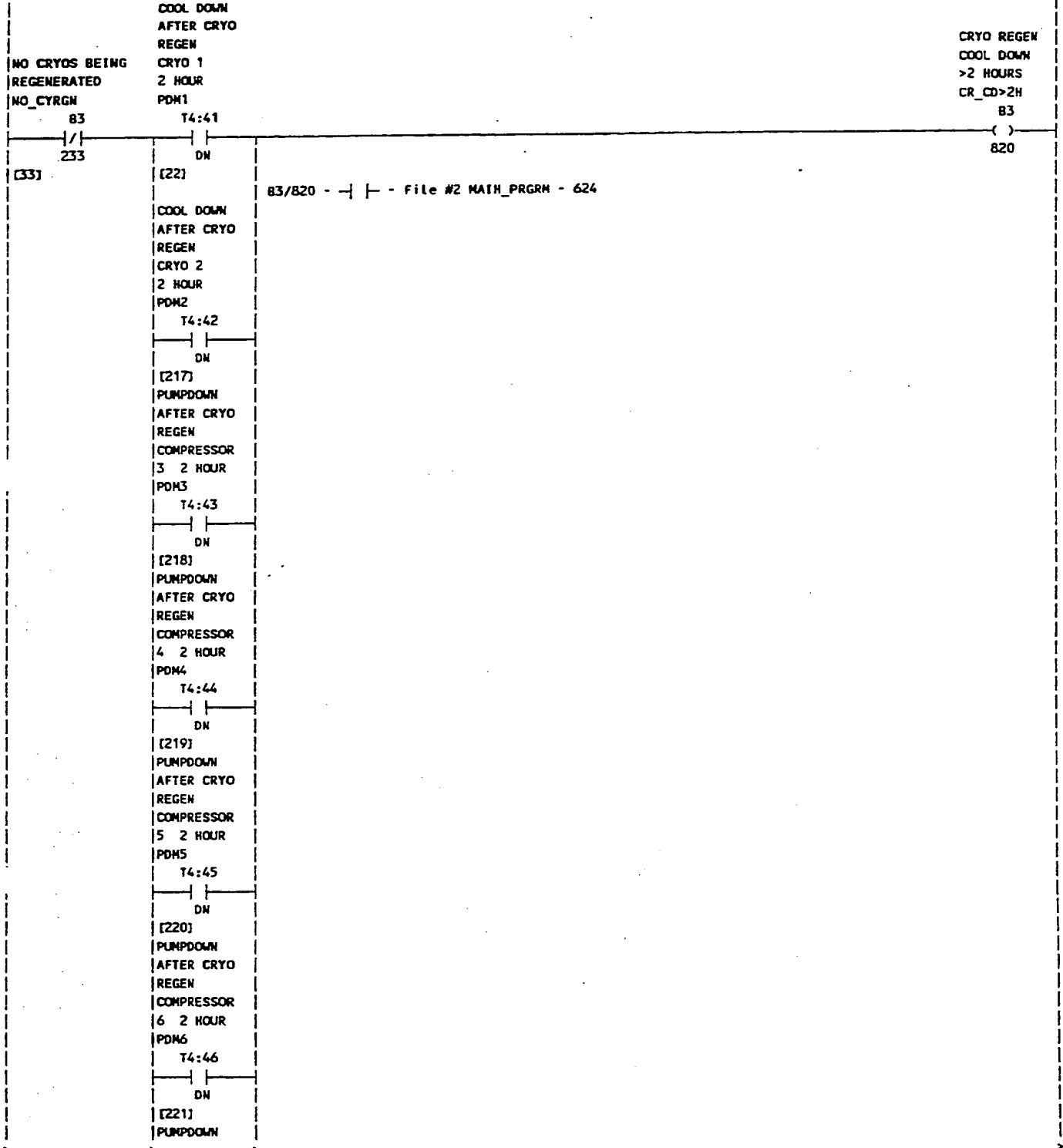


479

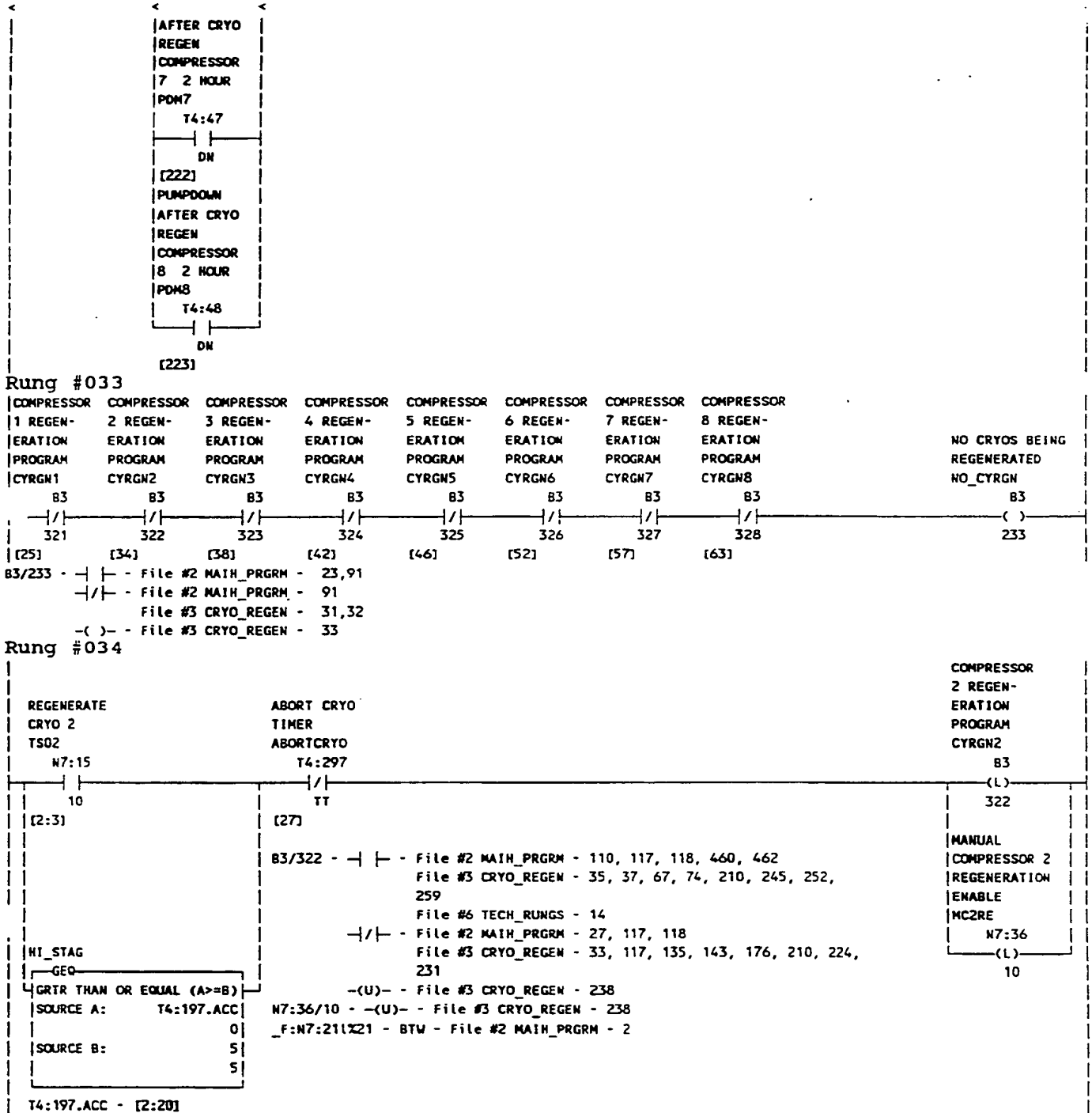
< 7 TIMER
DONE
5 MINUTE
CR7RUF_TMR
T4:177
| |
| DN
[169]
CR8RUF_TMR
T4:178
| |
| DN
[170]
CR9RUF_TMR
T4:179
| |
| DN
[171]
CR10RUF_TMR
T4:180
| |
| DN
[172]
CR11RUF_TMR
T4:181
| |
| DN
[174]

480

Rung #032



481



482

Rung #035

COMPRESSOR HEATER 2
2 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSE
CYRGN2 HV2S1

83 1:004
322 00

[34]

T4:62.TT - | | - File #3 CRYO_REGEN - 74, 81, 88
T4:342.ACC - LEQ - File #3 CRYO_REGEN - 37
T4:342.TT - | | - File #3 CRYO_REGEN - 36, 263
|/| - File #3 CRYO_REGEN - 264

REGEN COMP. 2
PULSE TIMER
CR2PT

TON
TIMER ON DELAY (EN)
TIMER: T4:62
BASE (SEC): 1.0 (DN)
PRESET: 1
ACCUM: 0

SIEVE TRAP
2 TIMER
S_TRAP_2

TON
TIMER ON DELAY (EN)
TIMER: T4:342
BASE (SEC): 1.0 (DN)
PRESET: 5400
ACCUM: 0

Rung #036

MECHANICAL
PUMP 2
ISOLATION
VALVE OPEN
MP2IVOP

S_TRAP_2
T4:342
TT 13

SIEVE TRAP
ISOLATION VALVE
2
SVIV2

0:010

()

01

[35]

0:010/01 - | | - File #3 CRYO_REGEN - 37

OPEN
CRYO ROUGH
VALVE 2
CR2
0:007

12

[164]

Rung #037

COMPRESSOR
2 REGEN-
ERATION
PROGRAM
CYRGN2

SIEVE TRAP
ISOLATION VALVE
2
SVIV2

SIEVE TRAP
HEATER 2
SVHTR2

0:010

83
322
[34]
S_TRAP_2
LEQ
LESS THAN OR EQUAL (A<=B)
SOURCE A: T4:342.ACC
SOURCE B: 3600
3600

0:010

01

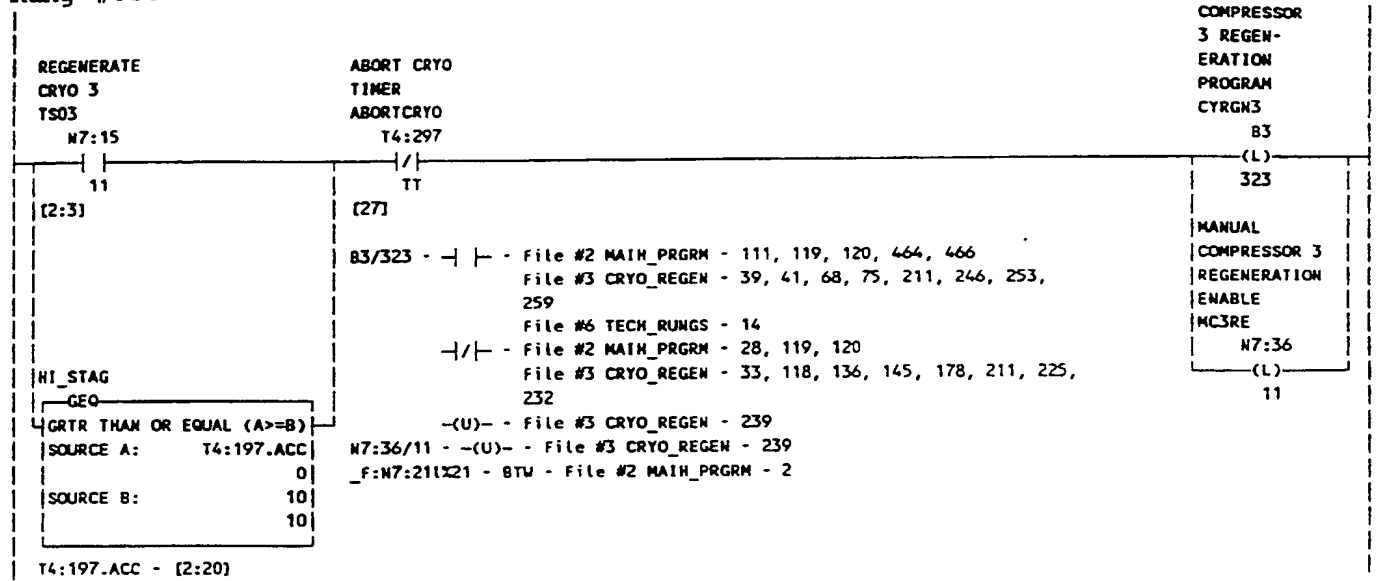
[36]

14

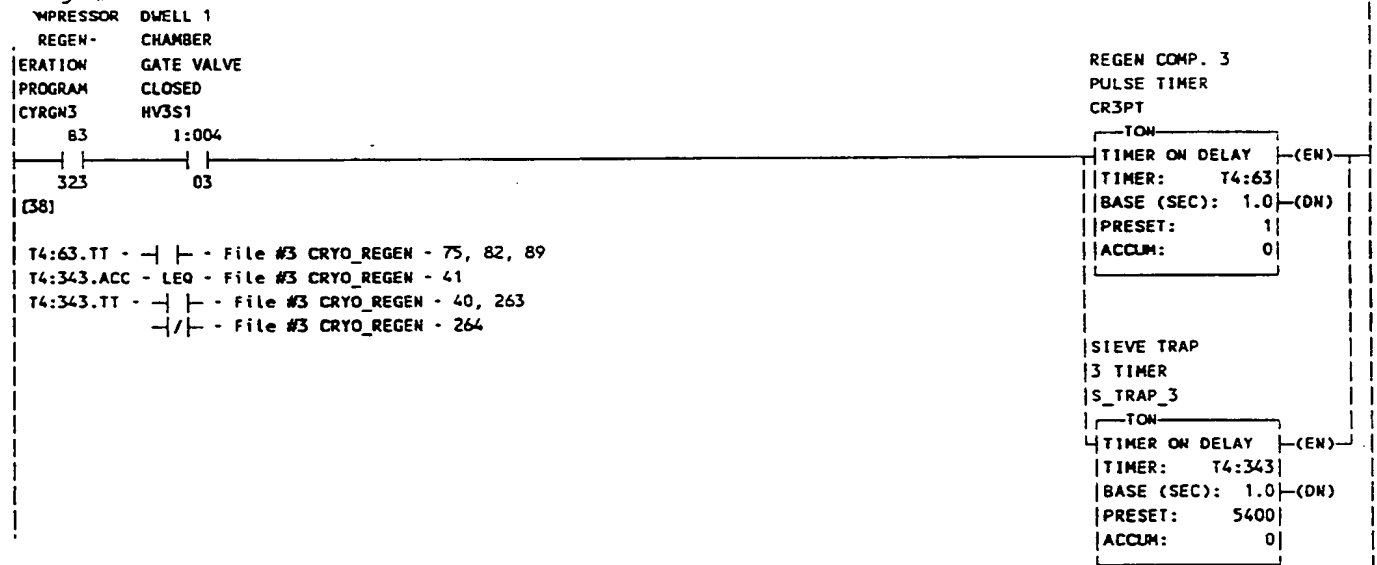
T4:342.ACC - [35]

483

Rung #038

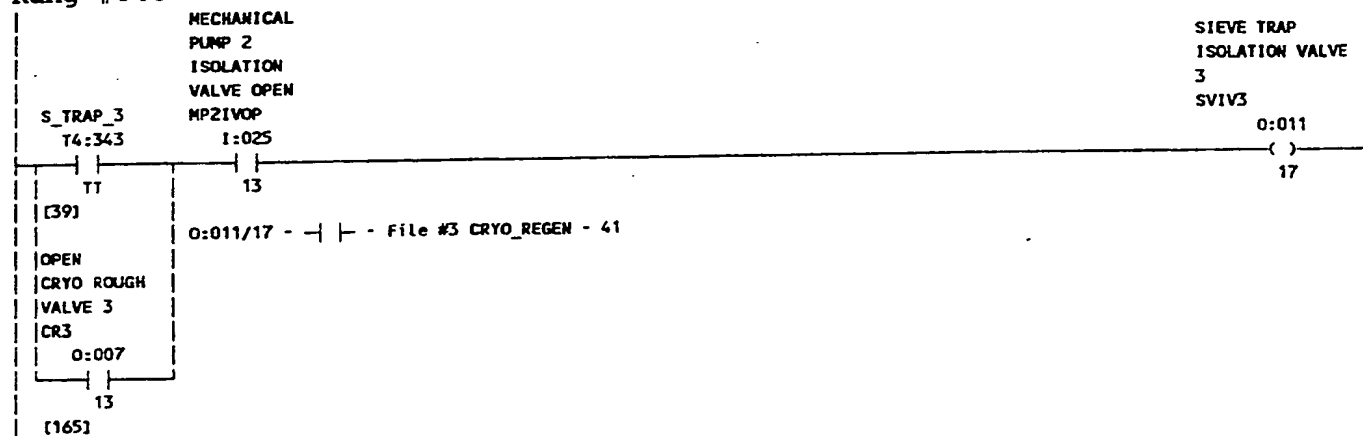


Rung #039

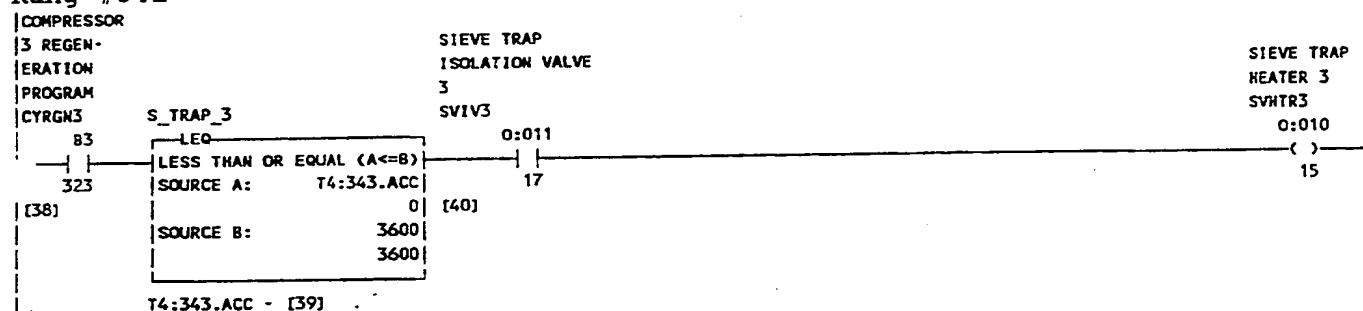


484

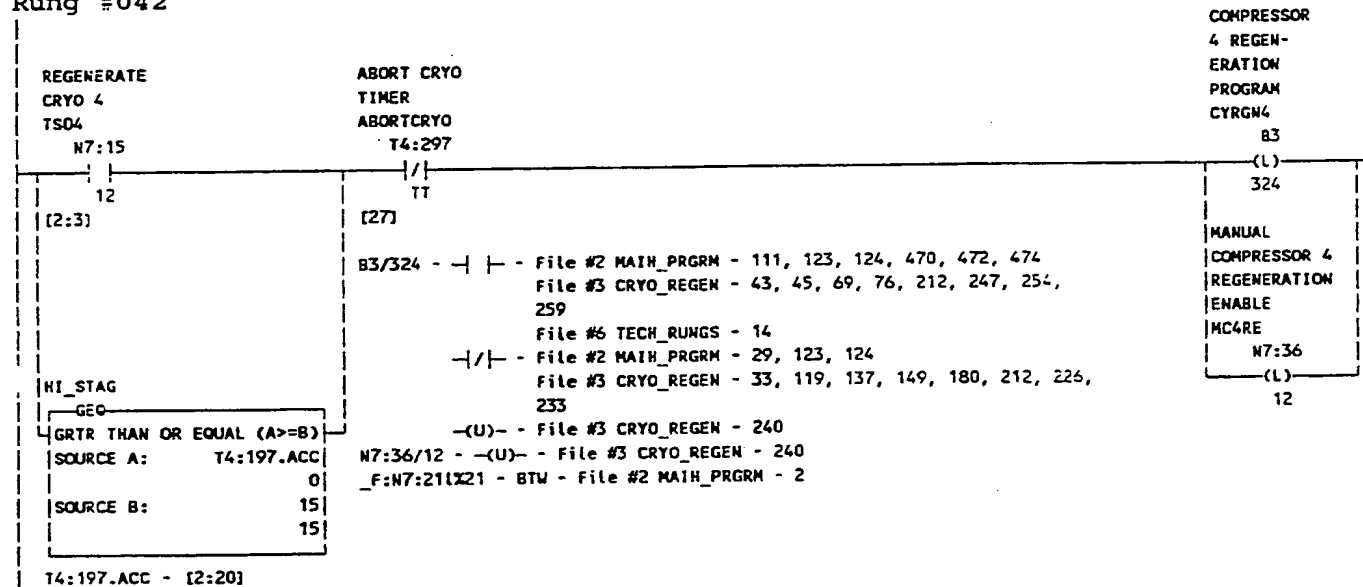
Rung #040



Rung #041



Rung #042



485

Rung #043

COMPRESSOR HEATER 3
4 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSED
CYRGN4 HVSS1

83 1:024
324 00

[42]

T4:64.TT - | | - File #3 CRYO_REGEN - 76, 83, 90
T4:344.ACC - LEQ - File #3 CRYO_REGEN - 45
T4:344.TT - | | - File #3 CRYO_REGEN - 44, 263
| | - File #3 CRYO_REGEN - 264

REGEN COMP. 4
PULSE TIMER
CR4PT

TIMER ON DELAY (EN)
TIMER: T4:64
BASE (SEC): 1.0 (DN)
PRESET: 1
ACCUM: 0

SIEVE TRAP
4 TIMER
S_TRAP_4

TIMER ON DELAY (EN)
TIMER: T4:344
BASE (SEC): 1.0 (DN)
PRESET: 5400
ACCUM: 0

Rung #044

MECHANICAL
PUMP 2
ISOLATION
VALVE OPEN
MP21VOP

S_TRAP_4
T4:344
TT 13
1:025

[43]

OPEN
CRYO ROUGH
VALVE 5
CR5
0:027
12

[166]

0:031/05 - | | - File #3 CRYO_REGEN - 45

SIEVE TRAP
ISOLATION VALVE
5
SVIV5

0:031
05

Rung #045

COMPRESSOR
4 REGEN-
ERATION
PROGRAM
CYRGN4

83
324

[42]

S_TRAP_4
LEQ
LESS THAN OR EQUAL (A<=B)
SOURCE A: T4:344.ACC
0
SOURCE B: 3600
3600

T4:344.ACC - [43]

SIEVE TRAP
ISOLATION VALVE
5
SVIV5

0:031
05

[44]

SIEVE TRAP
HEATER 5
SVHTR5

0:027
15

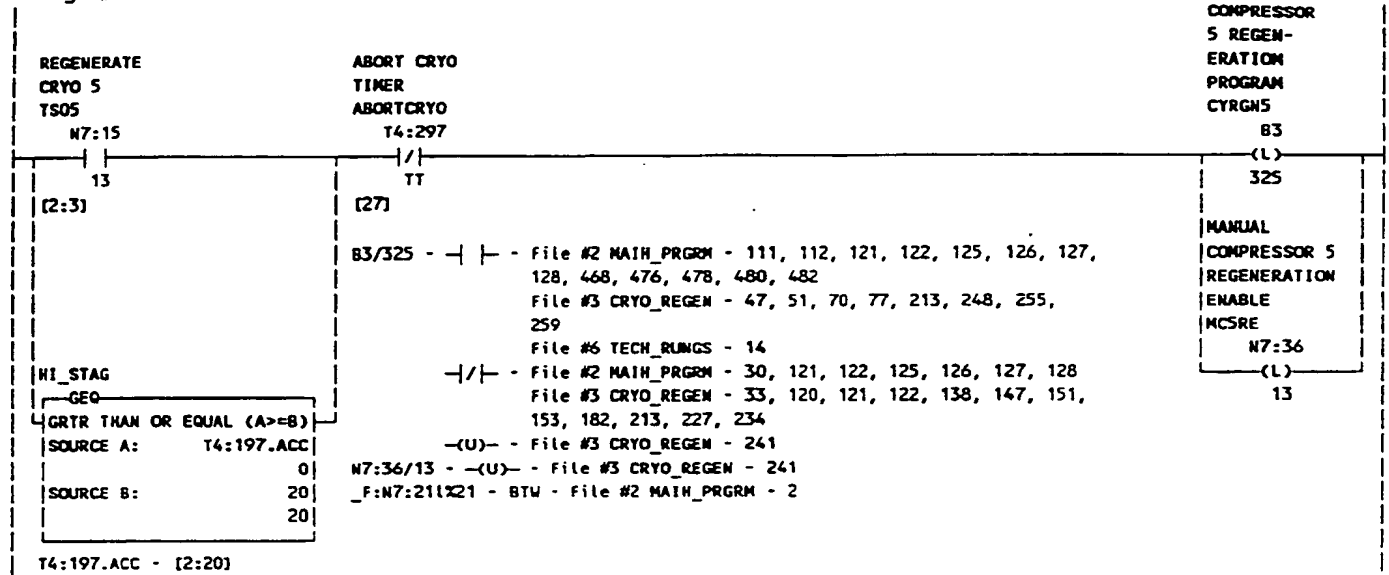
WO 92/17621

PCT/US92/00722

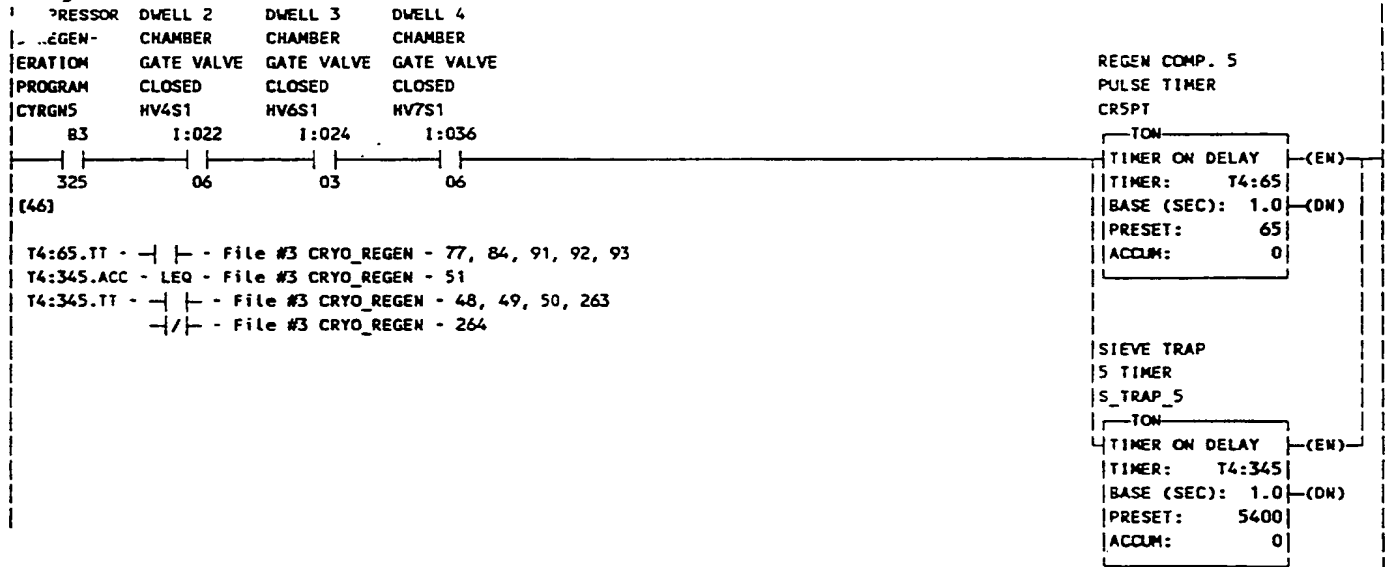
486

487

Rung #046

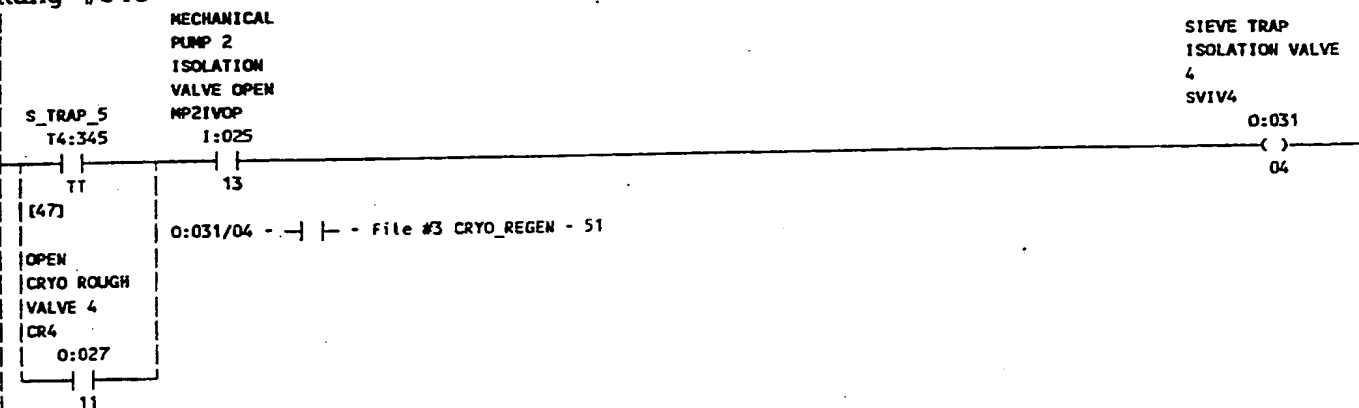


Rung #047

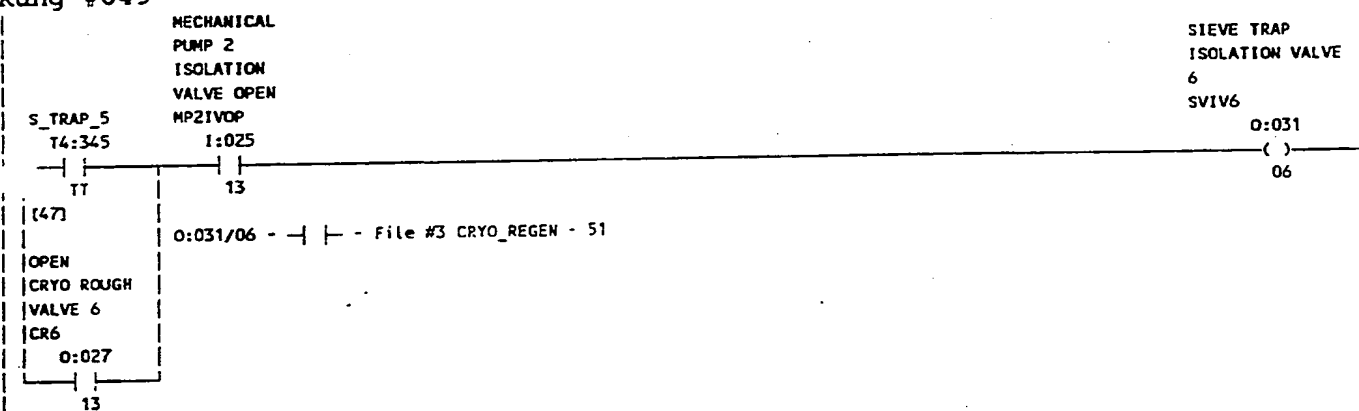


488

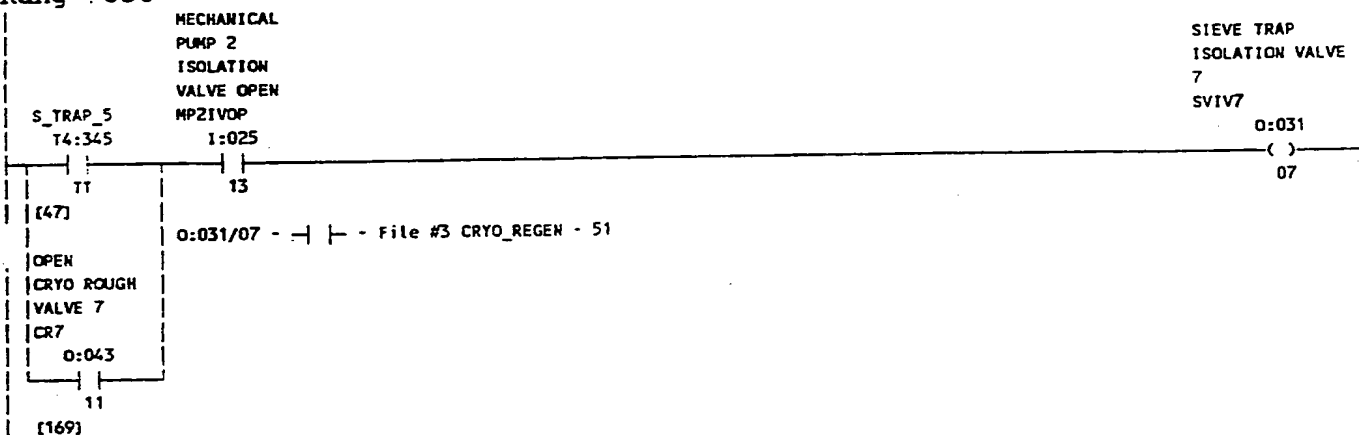
Rung #048



Rung #049

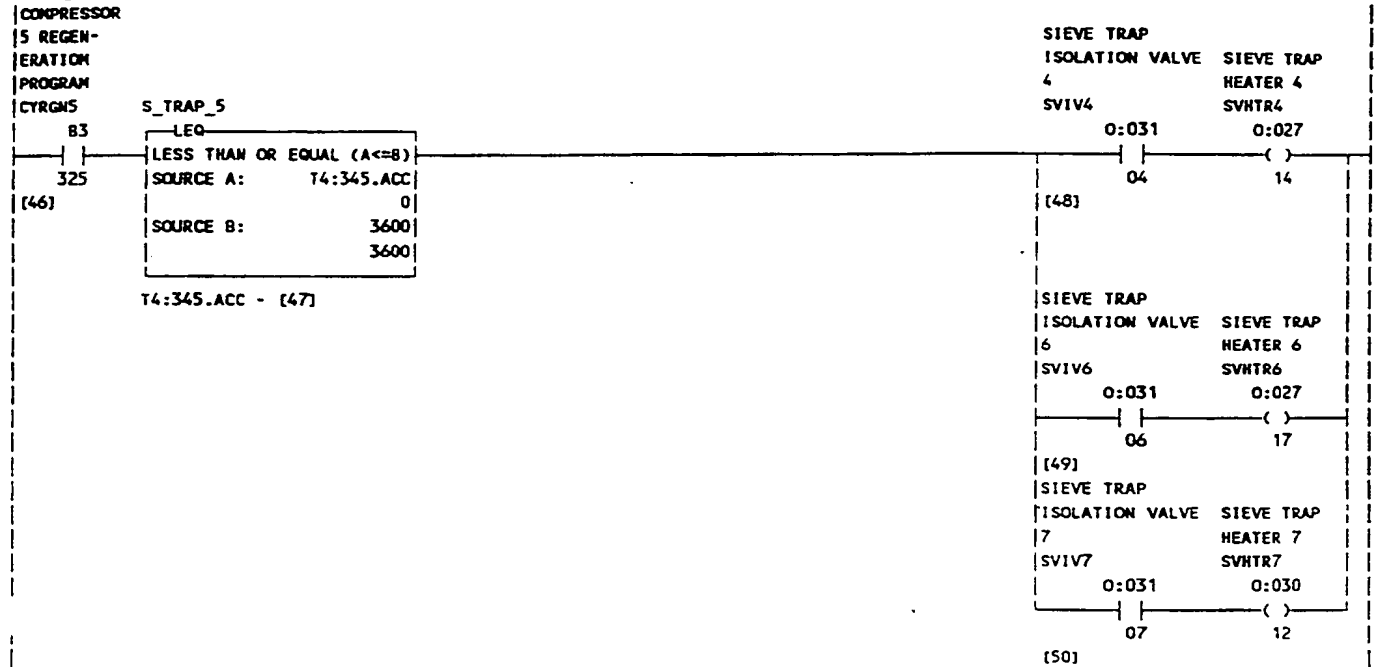


Rung #050

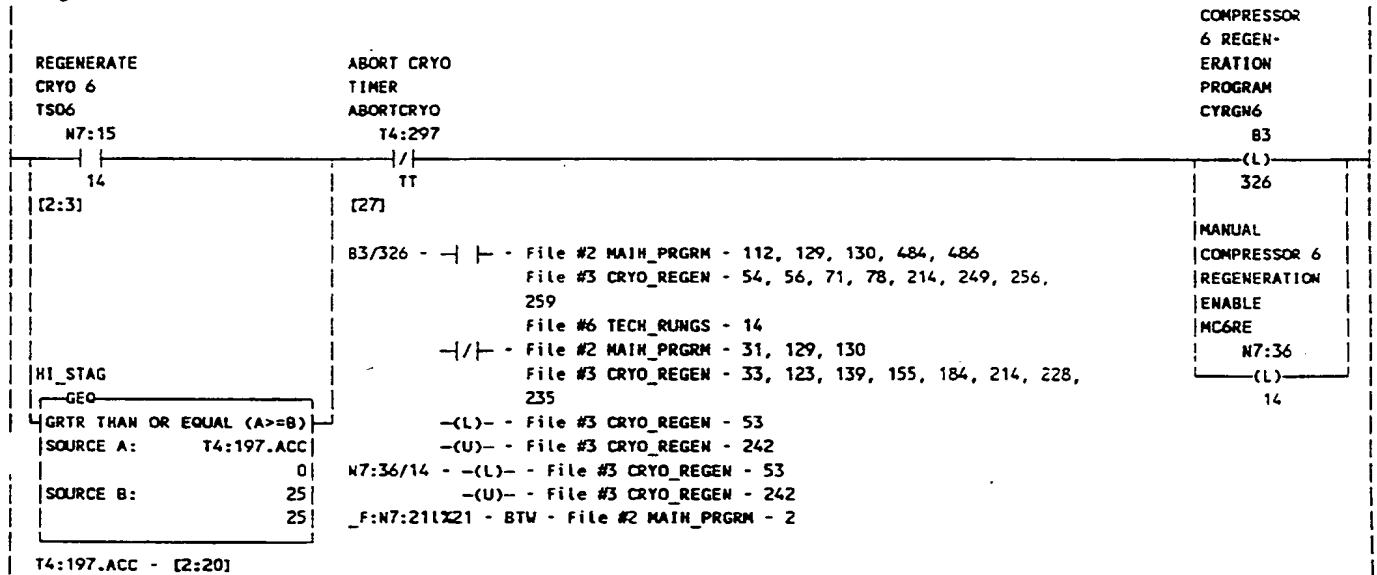


489

Rung #051

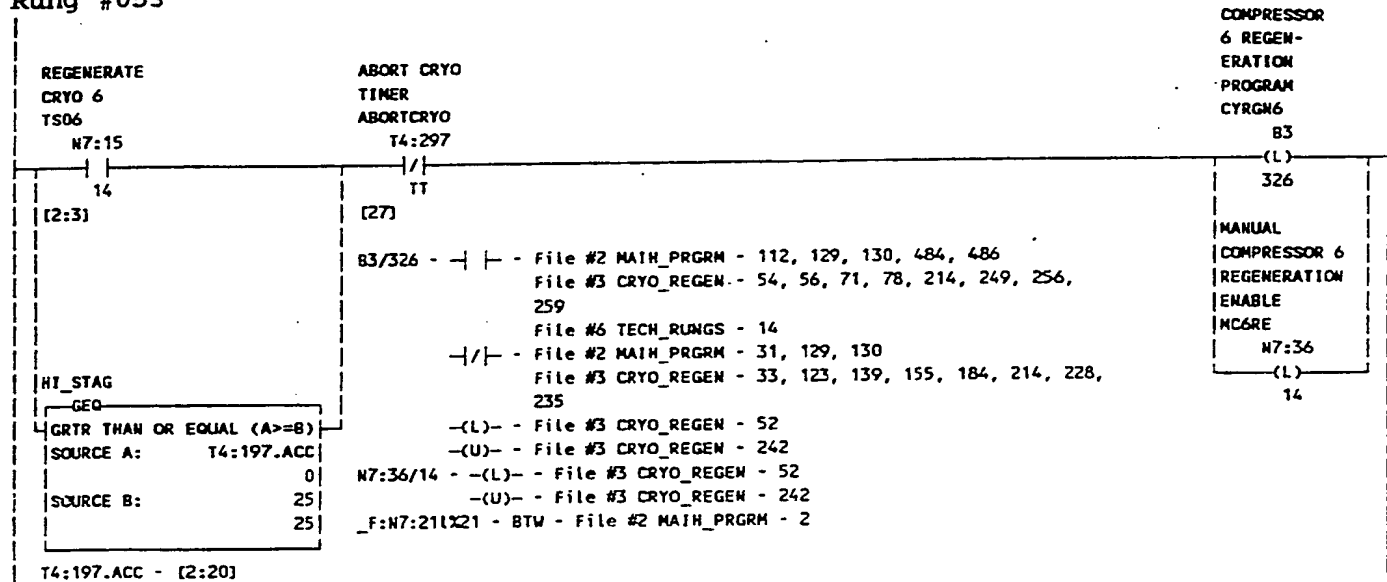


Rung #052

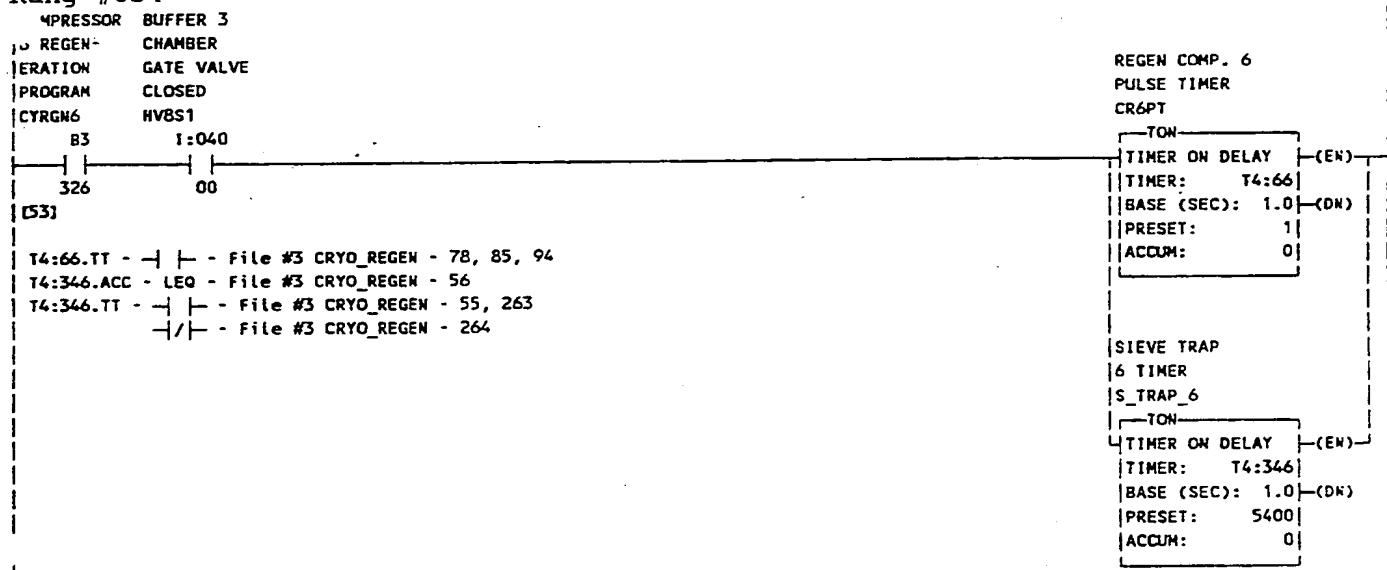


490

Rung #053

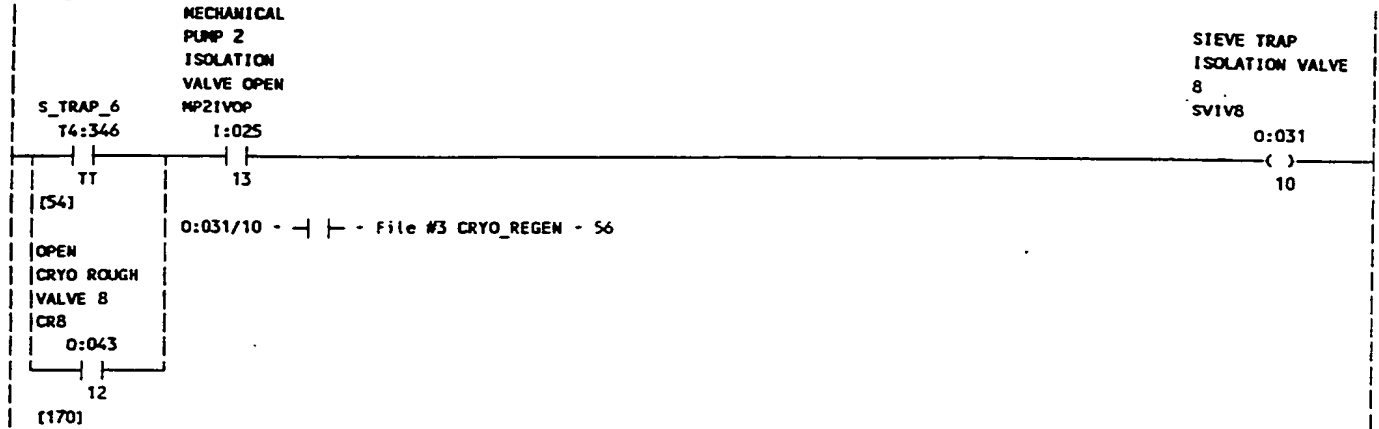


Rung #054

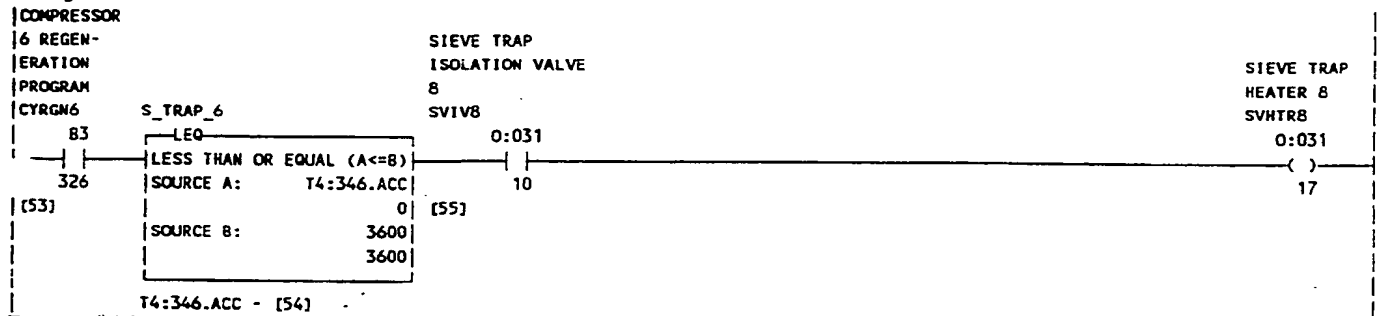


491

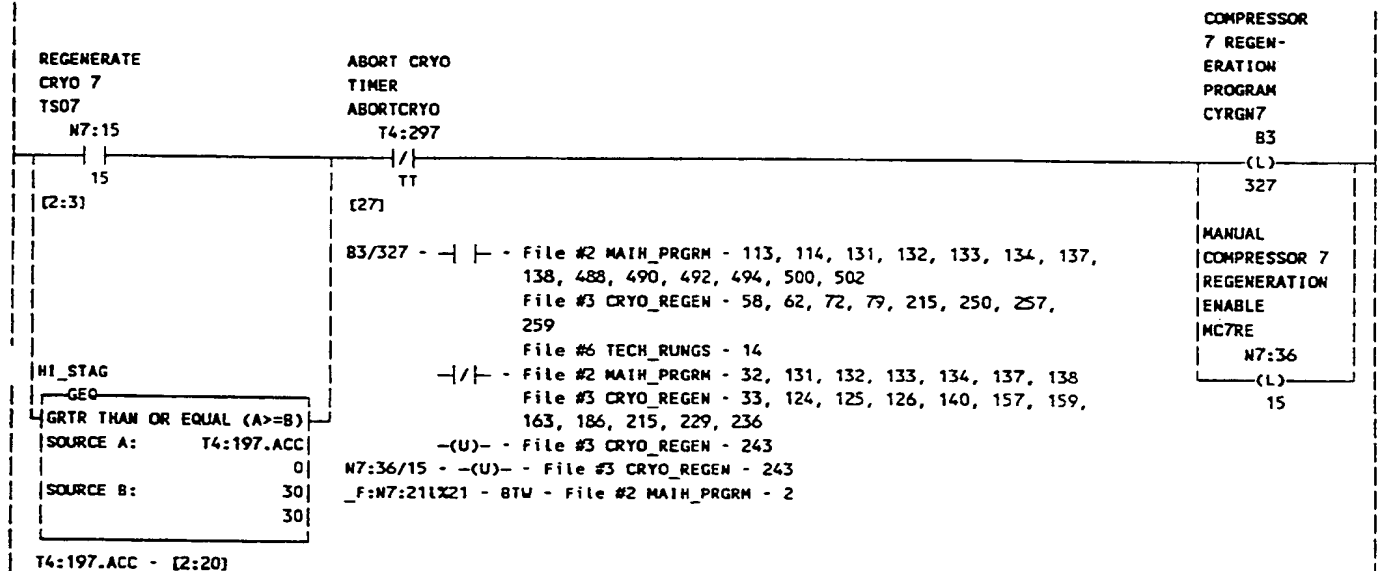
Rung #055



Rung #056



Rung #057



492

Rung #058

COMPRESSOR	DWELL 5	DWELL 6	EXITLOCK
7 REGEN- ERATION	CHAMBER GATE VALVE	CHAMBER GATE VALVE	CHAMBER GATE VALVE
PROGRAM	CLOSED	CLOSED	CLOSED
CYRGN7	HV9S1	HV10S1	HV12S1

83	1:040	1:052	1:054
327	03	06	03

[57]

T4:67.TT - | - File #3 CRYO_REGEN - 79, 86, 95, 96, 97
 T4:347.ACC - LEO - File #3 CRYO_REGEN - 62
 T4:347.TT - | - File #3 CRYO_REGEN - 59, 60, 61, 263
 -|/ - File #3 CRYO_REGEN - 264

REGEN COMP. 7
 PULSE TIMER
 CR7PT

TON	(EN)
TIMER ON DELAY	
TIMER: T4:67	
BASE (SEC): 1.0	(DN)
PRESET: 1	
ACCUM: 0	

SIEVE TRAP
 7 TIMER
 S_TRAP_7

TON	(EN)
TIMER ON DELAY	
TIMER: T4:347	
BASE (SEC): 1.0	(DN)
PRESET: 5400	
ACCUM: 0	

Rung #059

MECHANICAL
 PUMP 2
 ISOLATION
 VALVE OPEN
 MP21VOP

S_TRAP_7
 T4:347

TT	13

[58]

0:045/04 - | - File #3 CRYO_REGEN - 62

OPEN
 CRYO ROUGH
 VALVE 9
 CR9
 0:043

13

[171]

Rung #060

MECHANICAL
 PUMP 2
 ISOLATION
 VALVE OPEN
 MP21VOP

S_TRAP_7
 T4:347

TT	13

[58]

0:045/05 - | - File #3 CRYO_REGEN - 62

OPEN
 CRYO ROUGH
 VALVE 10
 CR10
 0:057

11

[172]

SIEVE TRAP
 ISOLATION VALVE
 9
 SVIV9

0:045

()

04

SIEVE TRAP
 ISOLATION VALVE
 10
 SVIV10

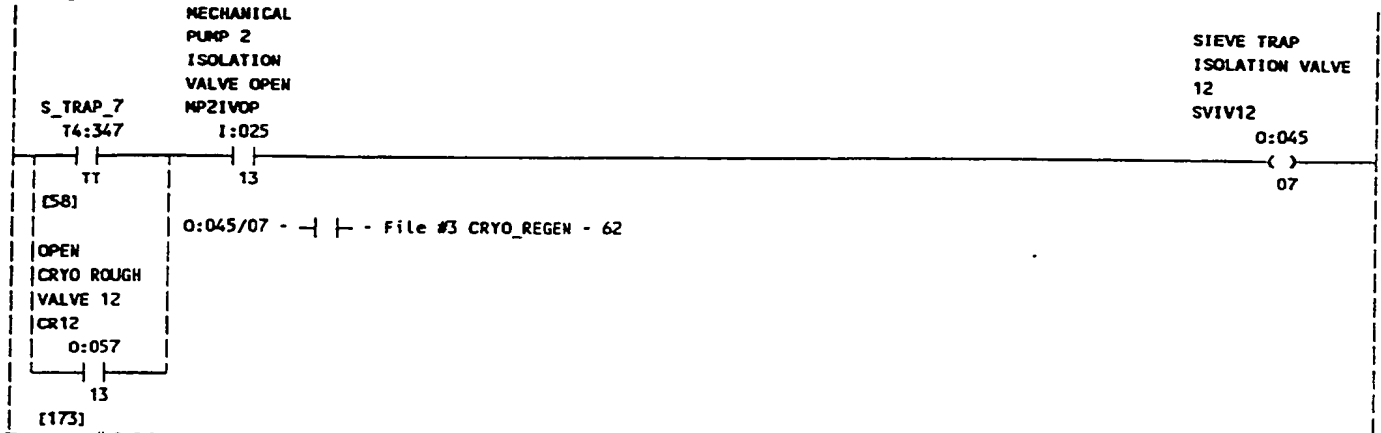
0:045

()

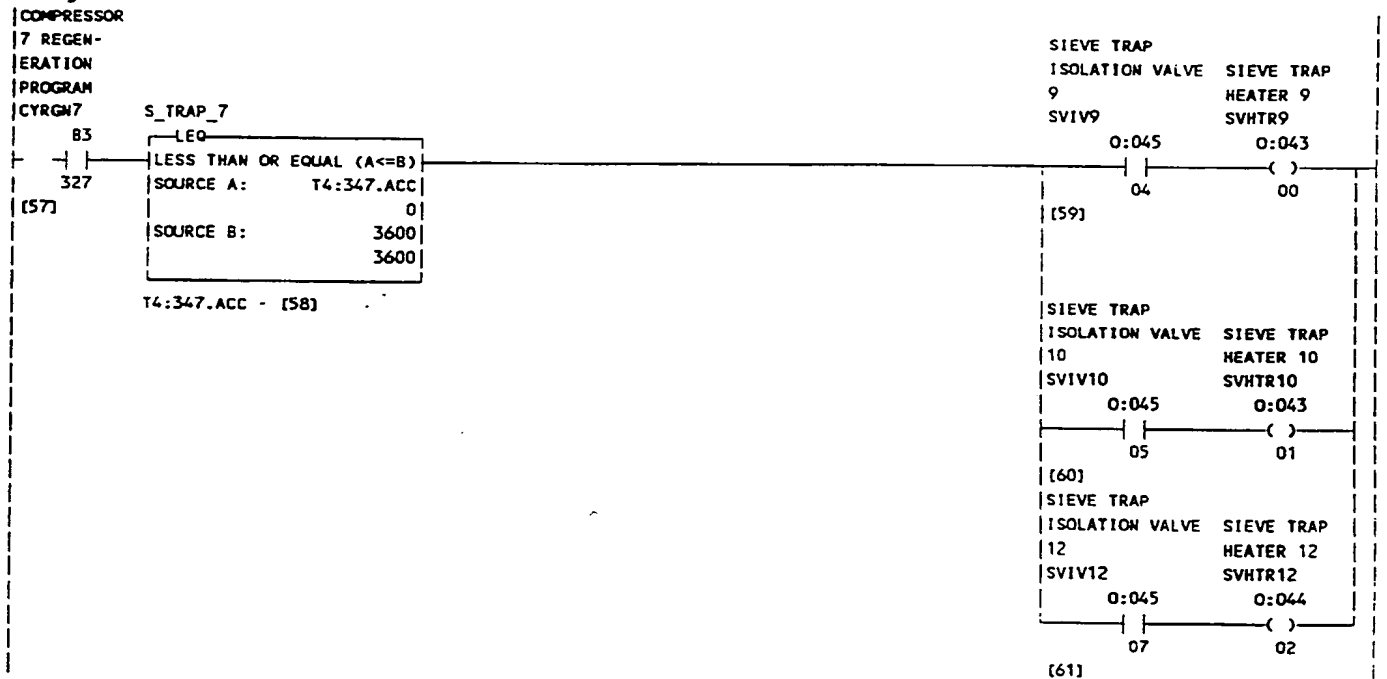
05

493

Rung #061

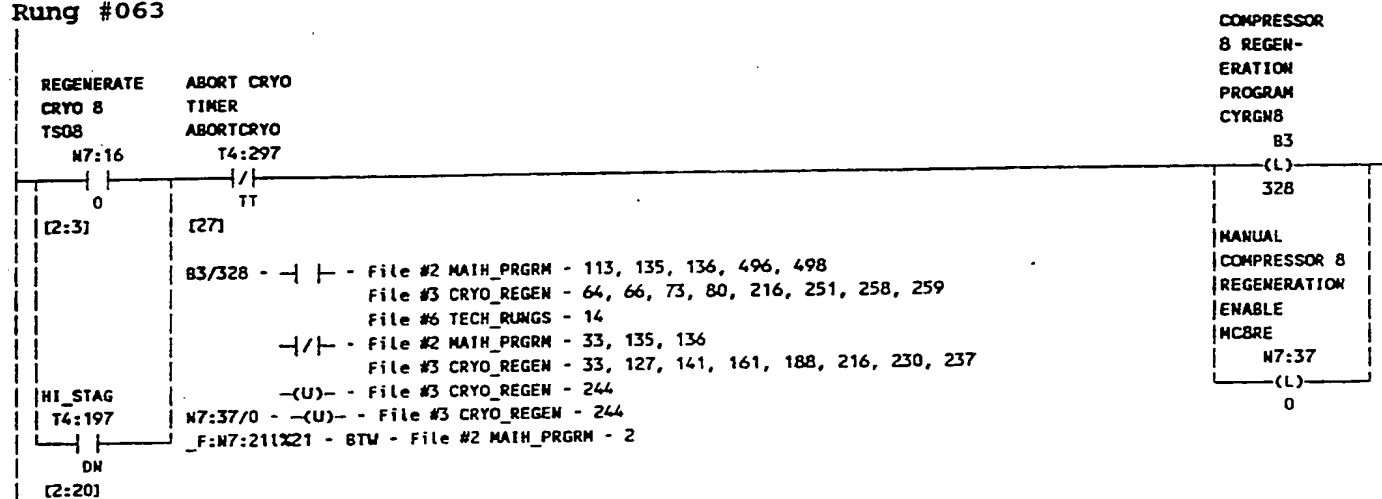


Rung #062

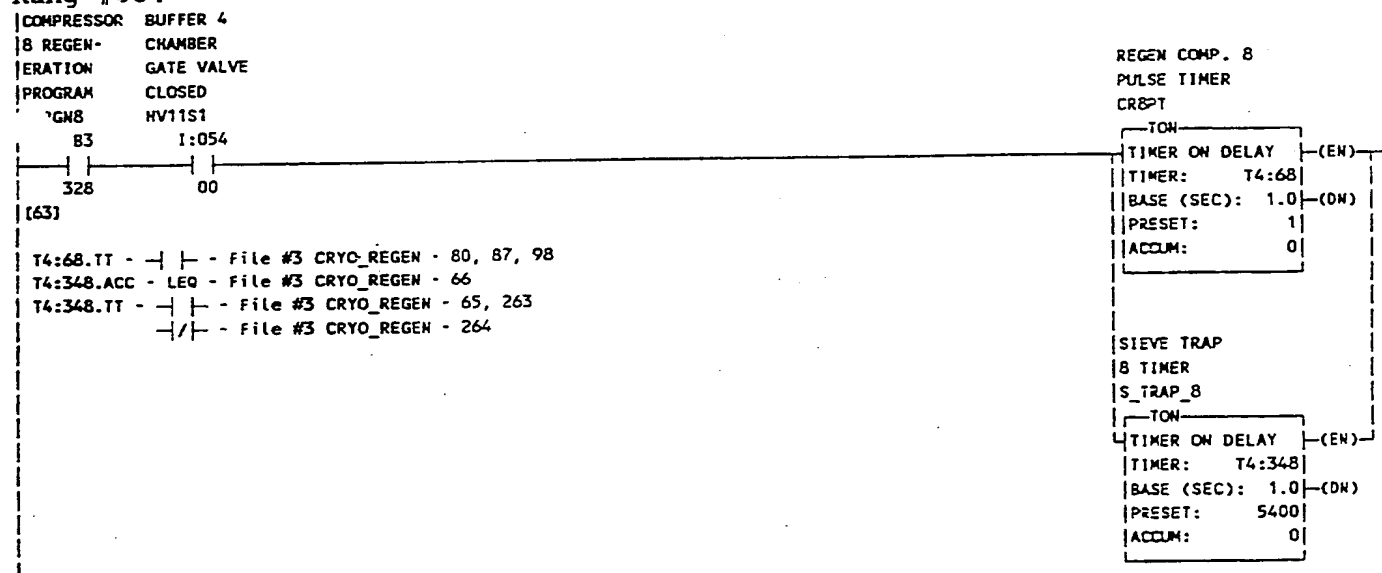


494

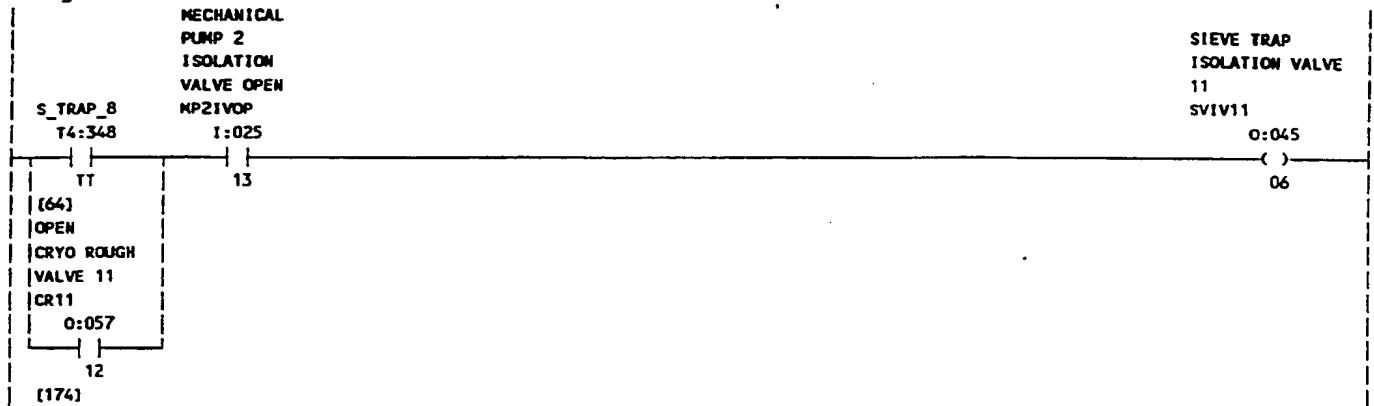
Rung #063



Rung #064



Rung #065



Rung #066



Rung #067



Rung #068



Rung #069



496

Rung #070

COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGN5

SCREEN
REGENERATION
CRYO 5
SCRRGN5

83

83

325

805

[46]

Rung #071

COMPRESSOR
6 REGEN-
ERATION
PROGRAM
CYRGN6

SCREEN
REGENERATION
CRYO 6
SCRRGN6

83

83

326

806

[53]

Rung #072

COMPRESSOR
7 REGEN-
ERATION
PROGRAM
CYRGN7

SCREEN
REGENERATION
CRYO 7
SCRRGN7

83

83

327

807

[57]

Rung #073

COMPRESSOR
8 REGEN-
ERATION
PROGRAM
CYRGN8

SCREEN
REGENERATION
CRYO 8
SCRRGN8

83

83

328

808

[63]

Rung #074

COMPRESSOR
2 REGEN-
ERATION CRYO REGEN
PROGRAM 2 PULSE
CYRGN2 CR2PT

PURGE 2
P2

83

83

322

(L)

T4:62

TT

632

[34]

[35]

B3/632 - | - File #3 CRYO_REGEN - 88,110,128

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 74

-(U)- File #3 CRYO_REGEN - 135

497

Rung #075

|COMPRESSOR

|3 REGEN-

|ERATION CRYO REGEN

|PROGRAM 3 PULSE

|CYRGN3 CR3PT

| 83 T4:63

| 323 TT

|[38] [39]

83/633 - | - File #3 CRYO_REGEN - 89,111,129

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 75

-(U)- File #3 CRYO_REGEN - 136

PURGE 3

P3

83

(L)

633

Rung #076

|COMPRESSOR

|4 REGEN-

|ERATION CRYO REGEN

|PROGRAM 4 PULSE

|CYRGN4 CR4PT

| 83 T4:64

| 324 TT

|[42] [43]

83/634 - | - File #3 CRYO_REGEN - 90,112,130

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 76

-(U)- File #3 CRYO_REGEN - 137

PURGE 4

P4

83

(L)

634

Rung #077

|COMPRESSOR

|5 REGEN-

|ERATION CRYO REGEN

|PROGRAM 5 PULSE

|CYRGN5 CR5PT

| 83 T4:65

| 325 TT

|[46] [47]

83/635 - | - File #3 CRYO_REGEN - 91,92,93,113,131

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 77

-(U)- File #3 CRYO_REGEN - 138

PURGE 5

P5

83

(L)

635

Rung #078

|COMPRESSOR

|6 REGEN-

|ERATION CRYO REGE]

|PROGRAM 6 PULSE

|CYRGN6 CR6PT

| 83 T4:66

| 326 TT

|[53] [54]

83/636 - | - File #3 CRYO_REGEN - 94,114,132

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 78

-(U)- File #3 CRYO_REGEN - 139

PURGE 6

P6

83

(L)

636

498

Rung #079

COMPRESSOR

7 REGEN-

ERATION CRYO REGEN

PROGRAM 7 PULSE

CYRGN7 CR7PT

83 T4:67

327 TT

[57] [58]

B3/637 - | | - File #3 CRYO_REGEN - 95,96,97,115,133

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 79

-(U)- File #3 CRYO_REGEN - 140

PURGE 7

P7

83

(L)

637

Rung #080

COMPRESSOR

8 REGEN-

ERATION CRYO REGEN

PROGRAM 8 PULSE

CYRGN8 CR8PT

83 T4:68

328 TT

[63] [64]

B3/638 - | | - File #3 CRYO_REGEN - 98,116,134

File #6 TECH_RUNGS - 15

-(L)- File #3 CRYO_REGEN - 80

-(U)- File #3 CRYO_REGEN - 141

PURGE 8

P8

83

(L)

638

Rung #081

CRYO REGEN

2 PULSE

CR2PT

T4:62

TT

[35]

O:010/05 - | | - File #2 MATH_PRGRM - 436, 440

File #3 CRYO_REGEN - 260

File #6 TECH_RUNGS - 19

-(L)- File #2 MAIN_PRGRM - 27

N7:34/6 - -(L)- File #2 MATH_PRGRM - 27

_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

N7:29/6 - -(U)- File #2 MAIN_PRGRM - 27

_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2

MAIN WATER ON

MAIN_H2O

1:002

/

07

MANUAL

CONTROL

STOP CRYO

COMPRESSOR

2

M-CY2-0

N7:8

6

[2:3]

ENABLE

CRYO

COMPRESSOR

2

CY2

O:010

(U)

05

MANUAL CRYO

COMPRESSOR 2

RUN

MCYC2RUN

N7:34

(U)

6

MANUAL CRYO

COMPRESSOR 2

STOP

MCYC2STOP

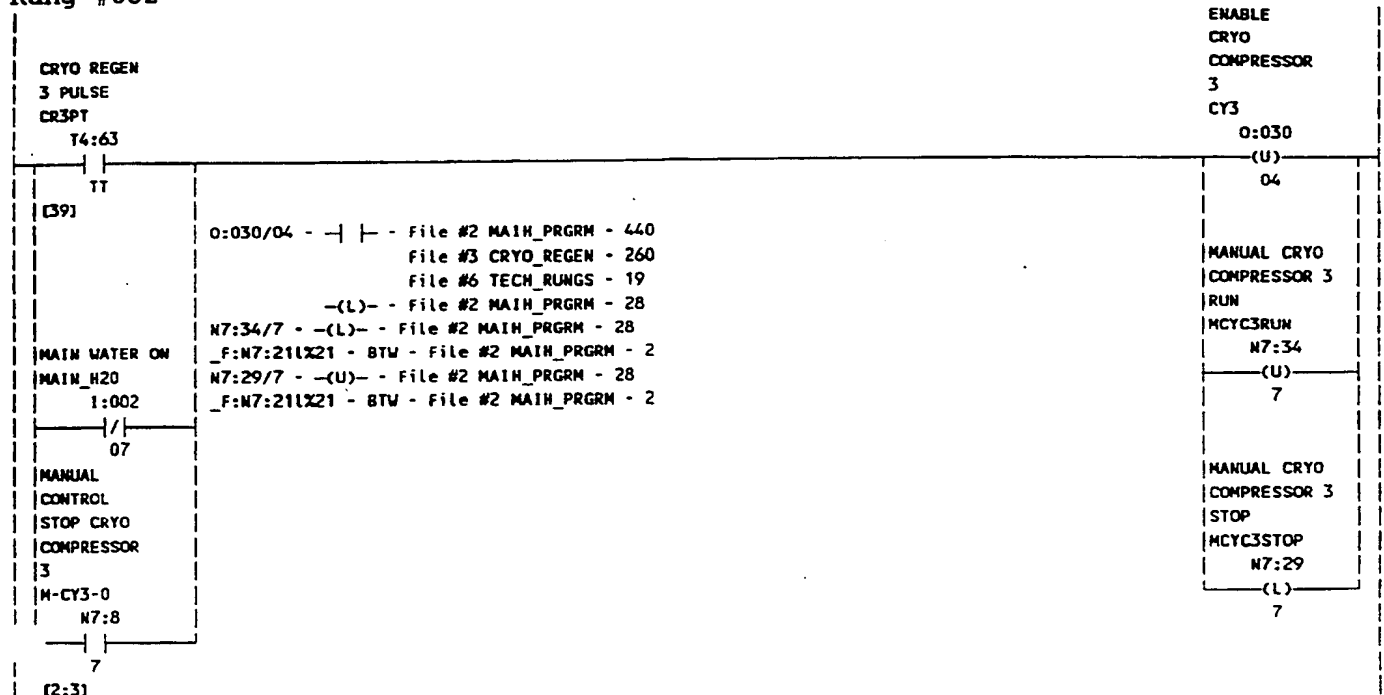
N7:29

(L)

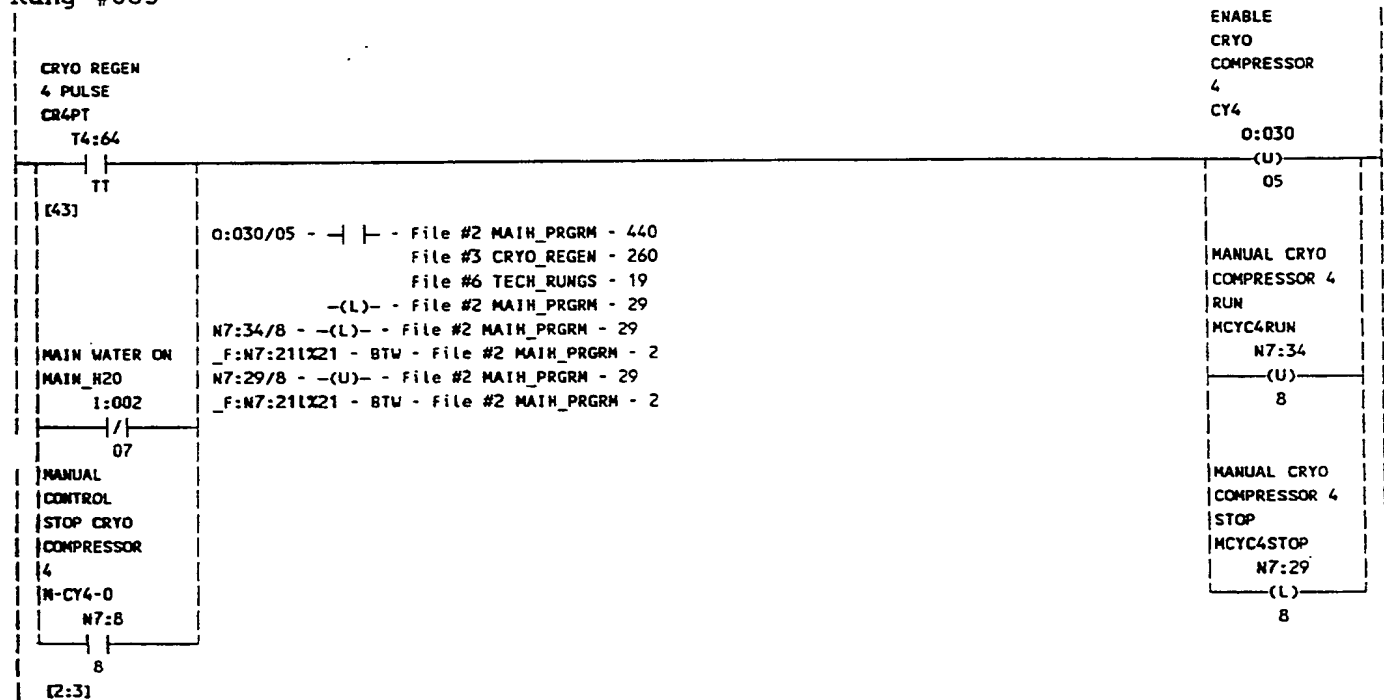
6

499

Rung #082



Rung #083



500

Rung #084

CRYO REGEN
5 PULSE
CR5PT
T4:65

TT
[47]

0:044/04 - | | - File #2 MAIN_PRGRM - 440, 444
File #3 CRYO_REGEN - 260
File #6 TECH_RUNGS - 19
-(L)- - File #2 MAIN_PRGRM - 30
N7:34/9 - -(L)- - File #2 MAIN_PRGRM - 30
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/9 - -(U)- - File #2 MAIN_PRGRM - 30
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MAIN WATER ON
MAIN_H2O
1:002
|/|
07

MANUAL
CONTROL
STOP CRYO
COMPRESSOR
5
M-CY5-0
N7:8

[2:3]

Rung #085

CRYO REGE
6 PULSE
CR6PT
T4:66

TT
[54]

0:044/05 - | | - File #2 MAIN_PRGRM - 444
File #3 CRYO_REGEN - 260
File #6 TECH_RUNGS - 19
-(L)- - File #2 MAIN_PRGRM - 31
N7:34/10 - -(L)- - File #2 MAIN_PRGRM - 31
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/10 - -(U)- - File #2 MAIN_PRGRM - 31
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MAIN WATER ON
MAIN_H2O
1:002
|/|
07

MANUAL
CONTROL
STOP CRYO
COMPRESSOR
6
M-CY6-0
N7:8

[2:3]

ENABLE
CRYO
COMPRESSOR
5
CY5

0:044
(U)
04

MANUAL CRYO
COMPRESSOR 5
RUN
MCYC5RUN
N7:34

(U)
9

MANUAL CRYO
COMPRESSOR 5
STOP
MCYC5STOP
N7:29

(L)
9

ENABLE
CRYO
COMPRESSOR
6
CY6

0:044
(U)
05

MANUAL CRYO
COMPRESSOR 6
RUN
MCYC6RUN
N7:34

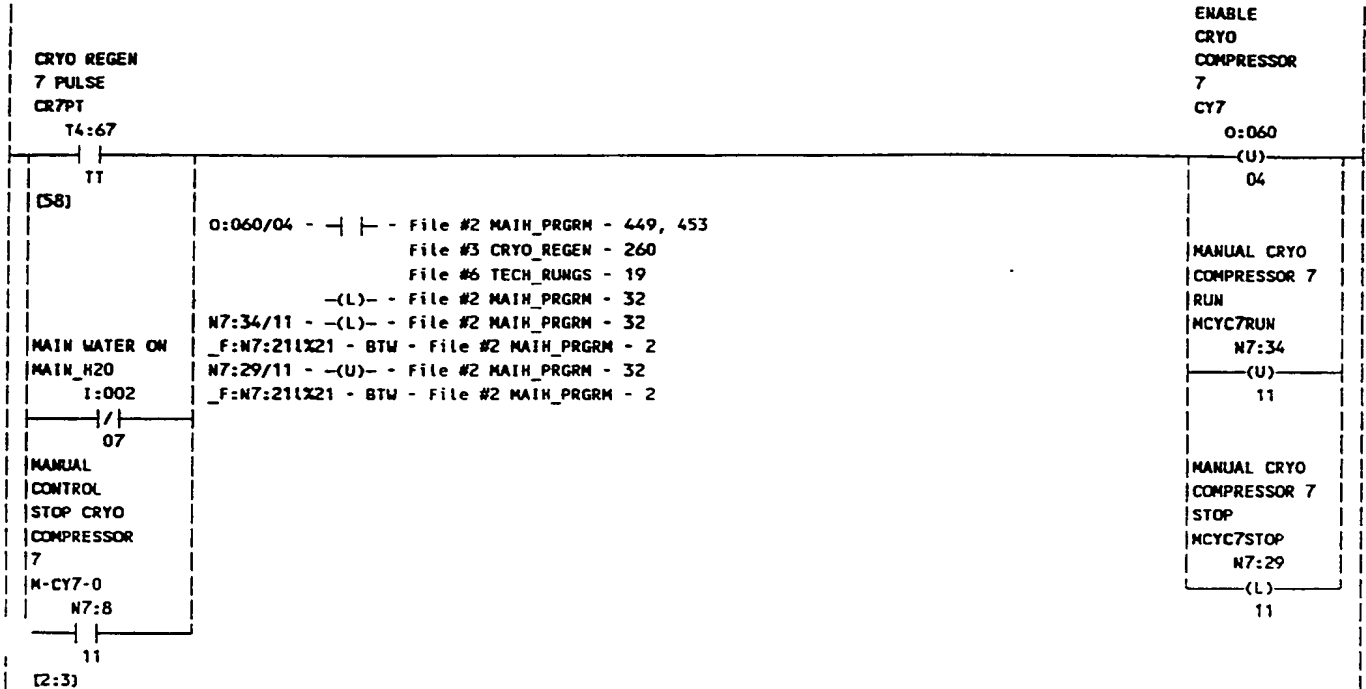
(U)
10

MANUAL CRYO
COMPRESSOR 6
STOP
MCYC6STOP
N7:29

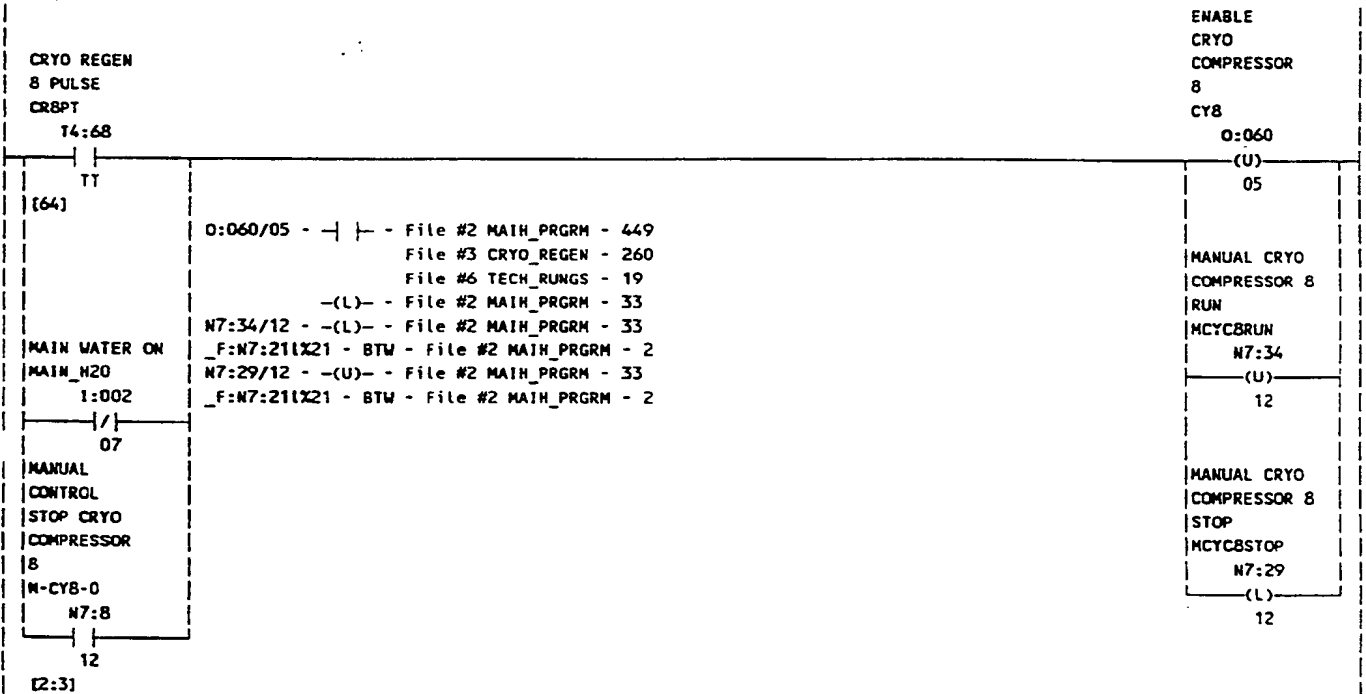
(L)
10

501

Rung #086

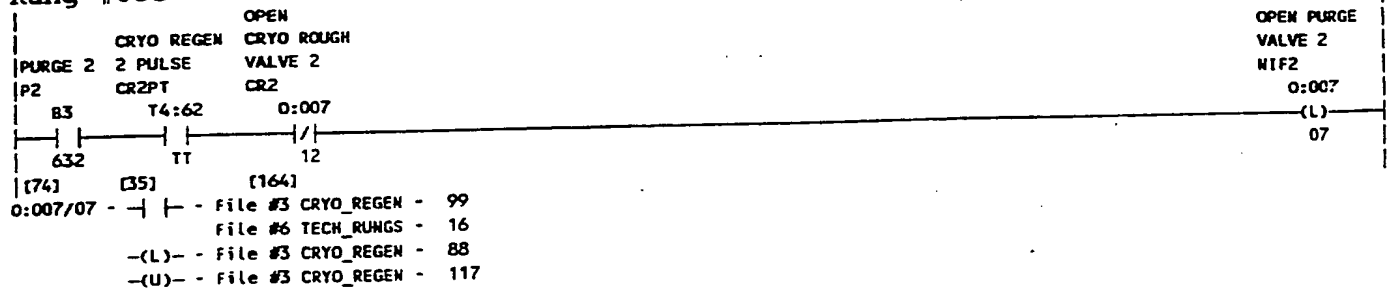


Rung #087



502

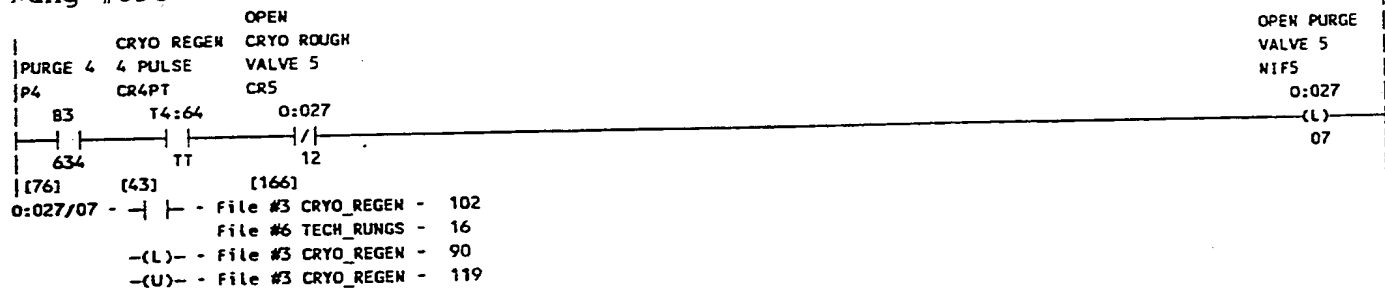
Rung #088



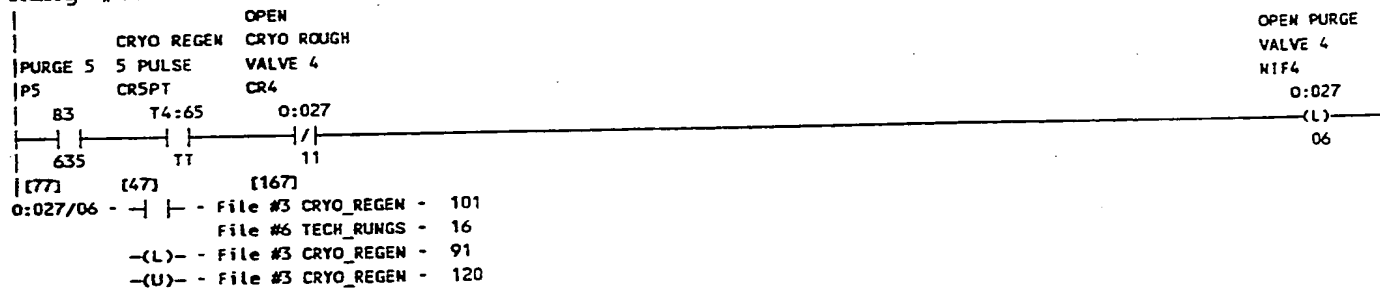
Rung #089



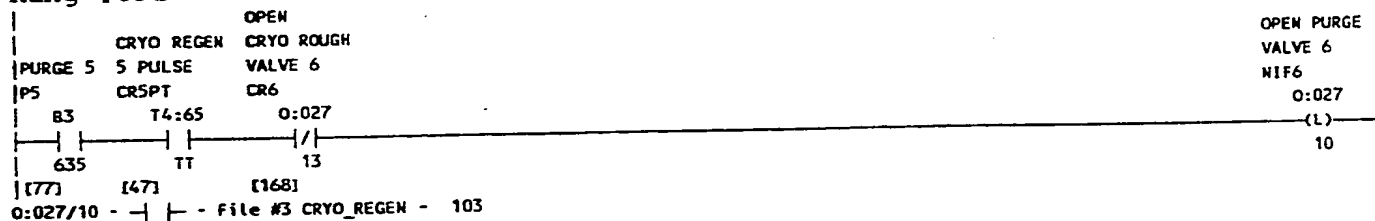
Rung #090



Rung #091



Rung #092



503

File #6 TECH_RUNGS - 16
 -(L)- File #3 CRYO_REGEN - 92
 -(U)- File #3 CRYO_REGEN - 121

Rung #093



0:043/06 - | | - File #3 CRYO_REGEN - 104
 File #6 TECH_RUNGS - 16
 -(L)- File #3 CRYO_REGEN - 93
 -(U)- File #3 CRYO_REGEN - 122

Rung #094



0:043/07 - | | - File #3 CRYO_REGEN - 106
 File #6 TECH_RUNGS - 16
 -(L)- File #3 CRYO_REGEN - 94
 -(U)- File #3 CRYO_REGEN - 123

Rung #095



0:043/10 - | | - File #3 CRYO_REGEN - 105
 File #6 TECH_RUNGS - 16
 -(L)- File #3 CRYO_REGEN - 95
 -(U)- File #3 CRYO_REGEN - 124

Rung #096



0:057/06 - | | - File #3 CRYO_REGEN - 107
 File #6 TECH_RUNGS - 16
 -(L)- File #3 CRYO_REGEN - 96
 -(U)- File #3 CRYO_REGEN - 125

504

Rung #097

	CRYO REGEN	CRYO ROUGH	OPEN		OPEN PURGE
PURGE 7	7 PULSE	VALVE 12			VALVE 12
P7	CR7PT	CR12			NIF12
					0:057
83	T4:67	0:057			(L)
637	TT	13			10
[79]	[58]	[173]			
0:057/10 - - File #3 CRYO_REGEN - 108					
File #6 TECH_RUNGS - 16					
-(L)- File #3 CRYO_REGEN - 97					
-(U)- File #3 CRYO_REGEN - 126					

Rung #098

	CRYO REGEN	CRYO ROUGH	OPEN		OPEN PURGE
PURGE 8	8 PULSE	VALVE 11			VALVE 11
P8	CR8PT	CR11			NIF11
					0:057
83	T4:68	0:057			(L)
638	TT	12			07
[80]	[64]	[174]			
0:057/07 - - File #3 CRYO_REGEN - 109					
File #6 TECH_RUNGS - 16					
-(L)- File #3 CRYO_REGEN - 98					
-(U)- File #3 CRYO_REGEN - 127					

Rung #099

OPEN PURGE		ENABLE
VALVE 2		PURGE
NIF2		HEATER 2
		NIF2
0:007		0:007
		()
07		04
[88]		
0:007/04 - - File #3 CRYO_REGEN - 110		
-() - File #3 CRYO_REGEN - 99		

Rung #100

OPEN PURGE		ENABLE
VALVE 3		PURGE
NIF3		HEATER 3
		NIF3
0:007		0:007
		()
10		05
[89]		
0:007/05 - - File #3 CRYO_REGEN - 111		
-() - File #3 CRYO_REGEN - 100		

Rung #101

OPEN PURGE		ENABLE
VALVE 4		PURGE
NIF4		HEATER 4
		NIF4
0:027		0:027
		()
06		03
[91]		
0:027/03 - - File #3 CRYO_REGEN - 113		
-() - File #3 CRYO_REGEN - 101		

505

Rung #102

OPEN PURGE
VALVE 5
NIF5

O:027

07

ENABLE
PURGE
HEATER 5
NIH5
O:027()
04

[90]

O:027/04 - | | - File #3 CRYO_REGEN - 112
-() - File #3 CRYO_REGEN - 102

Rung #103

OPEN PURGE
VALVE 6
NIF6

O:027

10

ENABLE
PURGE
HEATER 6
NIH6
O:027()
05

[92]

O:027/05 - | | - File #3 CRYO_REGEN - 113
-() - File #3 CRYO_REGEN - 103

Rung #104

OPEN PURGE
VALVE 7
NIF7

O:043

06

ENABLE
PURGE
HEATER 7
NIH7
O:043()
03

[93]

O:043/03 - | | - File #3 CRYO_REGEN - 113
-() - File #3 CRYO_REGEN - 104

Rung #105

OPEN PURGE
VALVE 9
NIF9

O:043

10

ENABLE
PURGE
HEATER 9
NIH9
O:043()
05

[95]

O:043/05 - | | - File #3 CRYO_REGEN - 115
-() - File #3 CRYO_REGEN - 105

Rung #106

OPEN PURGE
VALVE 8
NIF8

O:043

07

ENABLE
PURGE
HEATER 8
NIH8
O:043()
04

[94]

O:043/04 - | | - File #3 CRYO_REGEN - 114
-() - File #3 CRYO_REGEN - 106

506

Rung #107

OPEN PURGE
VALVE 10
NIF10

0:057

06

ENABLE
PURGE
HEATER 10
NIH10

0:057

03

[96]
0:057/03 - | | - File #3 CRYO_REGEN - 115
- () - File #3 CRYO_REGEN - 107

Rung #108

OPEN PURGE
VALVE 12
NIF12

0:057

10

ENABLE
PURGE
HEATER 12
NIH12

0:057

05

[97]
0:057/05 - | | - File #3 CRYO_REGEN - 115
- () - File #3 CRYO_REGEN - 108

Rung #109

OPEN PURGE
VALVE 11
NIF11

0:057

07

ENABLE
PURGE
HEATER 11
NIH11

0:057

04

[98]
0:057/04 - | | - File #3 CRYO_REGEN - 116
- () - File #3 CRYO_REGEN - 109

Rung #110

ENABLE CRYO 2 PURGE
PURGE TEMPERATUR TIMER
PURGE 2 HEATER 2 =>290K DEFEAT
P2 NIH2 CY2TMP290 PG_DEFEAT

83

0:007

83

83

632

04

514

288

[135]

[99]

PURGE TIME
MONITOR
COMPRESSOR 2
PGC2TON
TIMER ON DELAY (EN)
TIMER: T4:22
BASE (SEC): 1.0 (DN)
PRESET: 7200
ACCUM: 0T4:22.ACC - GEQ - File #3 CRYO_REGEN - 252
T4:22.DN - | | - File #3 CRYO_REGEN - 117,128,262
T4:22.TT - | | - File #6 TECH_RUNGS - 15

Rung #111

ENABLE CRYO 3 PURGE
PURGE TEMPERATUR TIMER
PURGE 3 HEATER 3 =>290K DEFEAT
P3 NIH3 CY3TMP290 PG_DEFEAT

83

0:007

83

83

633

05

515

288

[136]

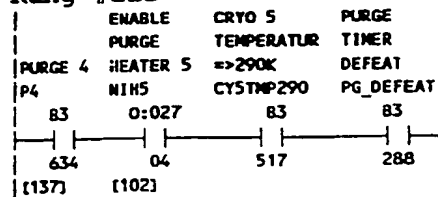
[100]

PURGE TIME
MONITOR
COMPRESSOR 3
PGC3TON
TIMER ON DELAY (EN)
TIMER: T4:23
BASE (SEC): 1.0 (DN)
PRESET: 7200
ACCUM: 0T4:23.ACC - GEQ - File #3 CRYO_REGEN - 253
T4:23.DN - | | - File #3 CRYO_REGEN - 118,129,262

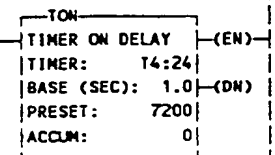
507

T4:23.TT - | | - File #6 TECH_RUNGS - 15

Rung #112



PURGE TIME
MONITOR
COMPRESSOR 4
PGC4

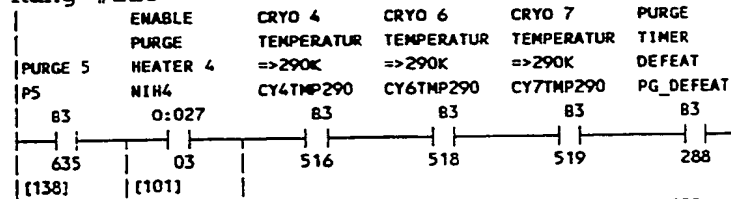


T4:24.ACC - GEQ - File #3 CRYO_REGEN - 254

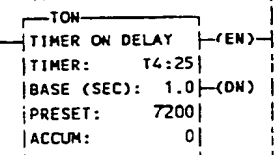
T4:24.DN - | | - File #3 CRYO_REGEN - 119,130,262

T4:24.TT - | | - File #6 TECH_RUNGS - 15

Rung #113



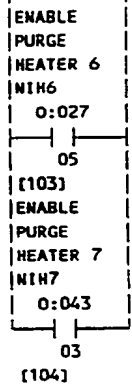
PURGE TIME
MONITOR
COMPRESSOR 5
PGC5



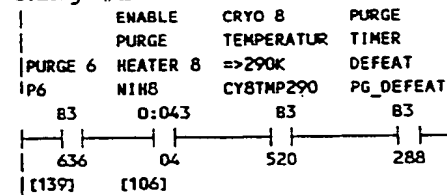
T4:25.ACC - GEQ - File #3 CRYO_REGEN - 255

T4:25.DN - | | - File #3 CRYO_REGEN - 120, 121, 122, 131, 262

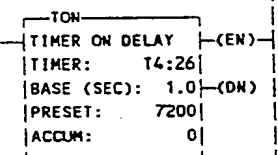
T4:25.TT - | | - File #6 TECH_RUNGS - 15



Rung #114



PURGE TIME
MONITOR
COMPRESSOR 6
PGC6



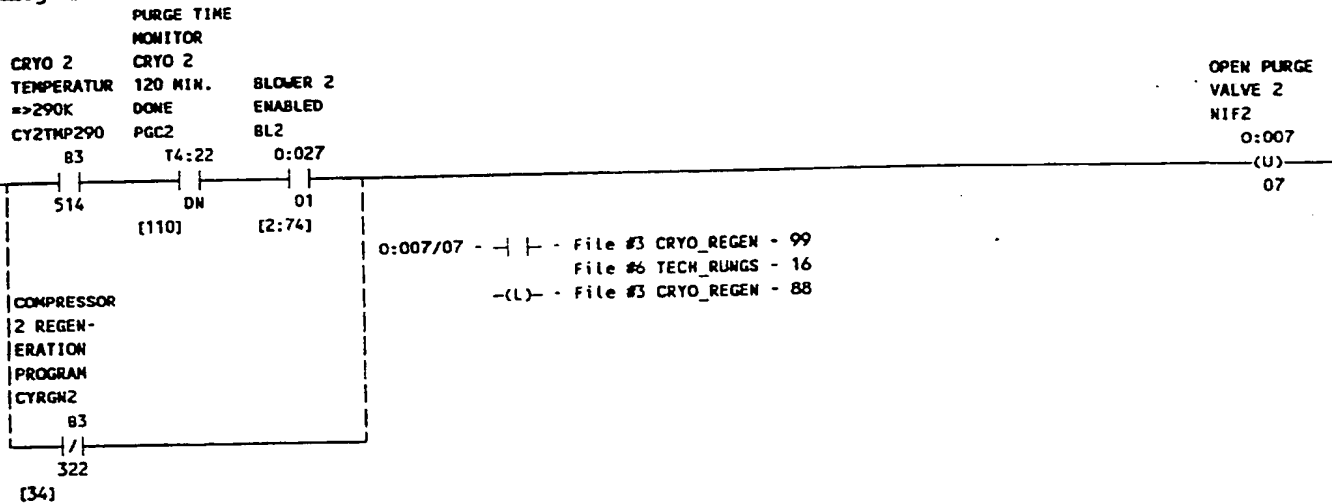
T4:26.ACC - GEQ - File #3 CRYO_REGEN - 256

T4:26.DN - | | - File #3 CRYO_REGEN - 123,132,262

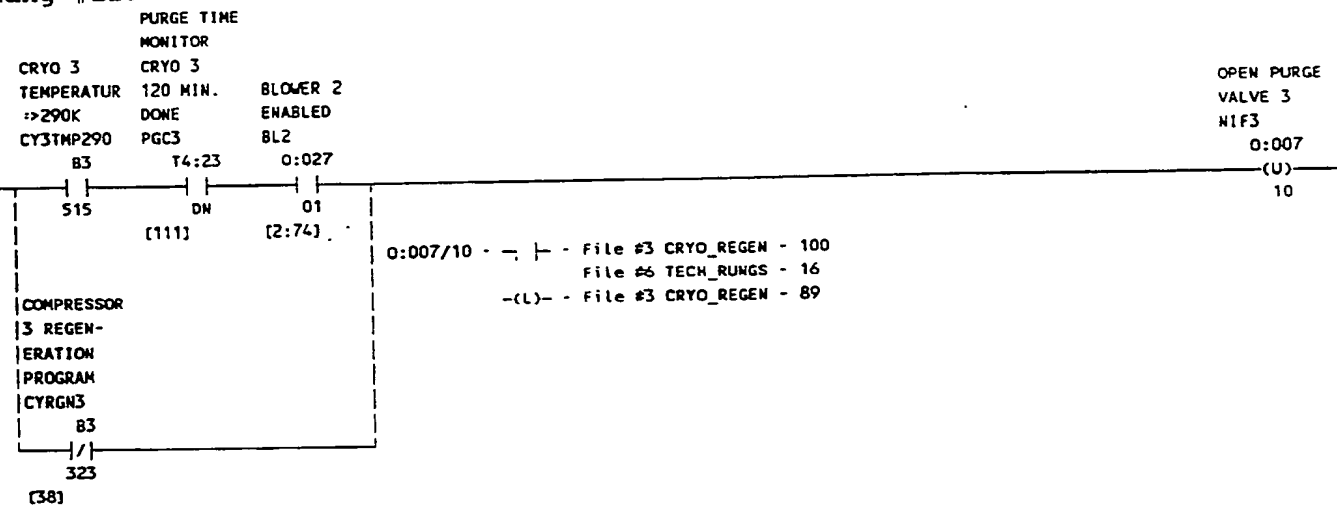
T4:26.TT - | | - File #6 TECH_RUNGS - 15

509

Rung #117

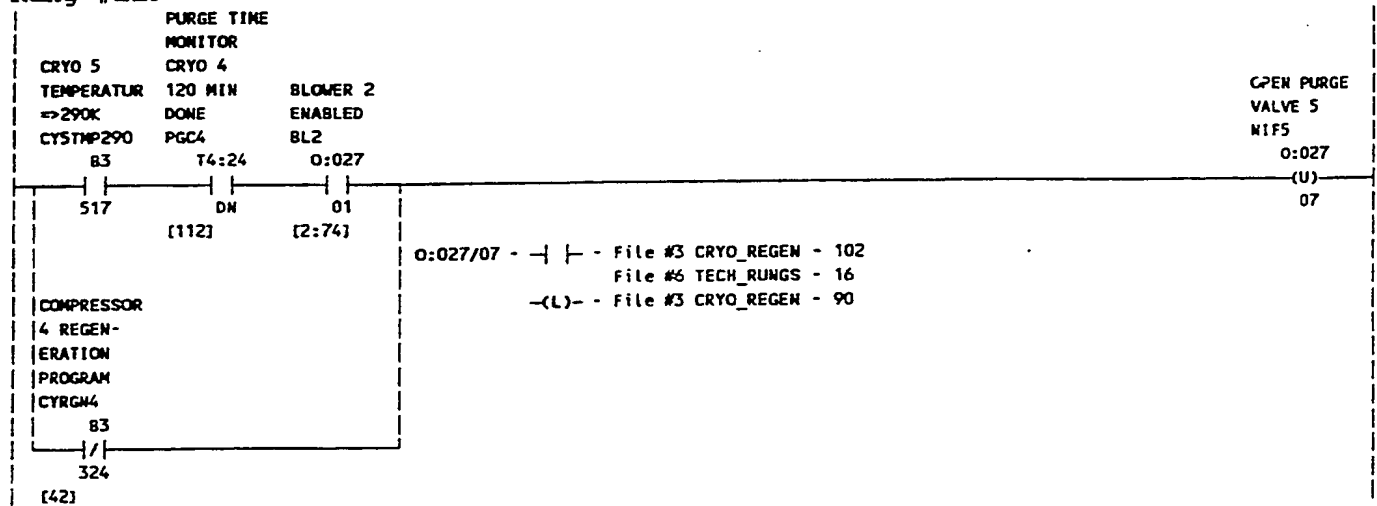


Rung #118

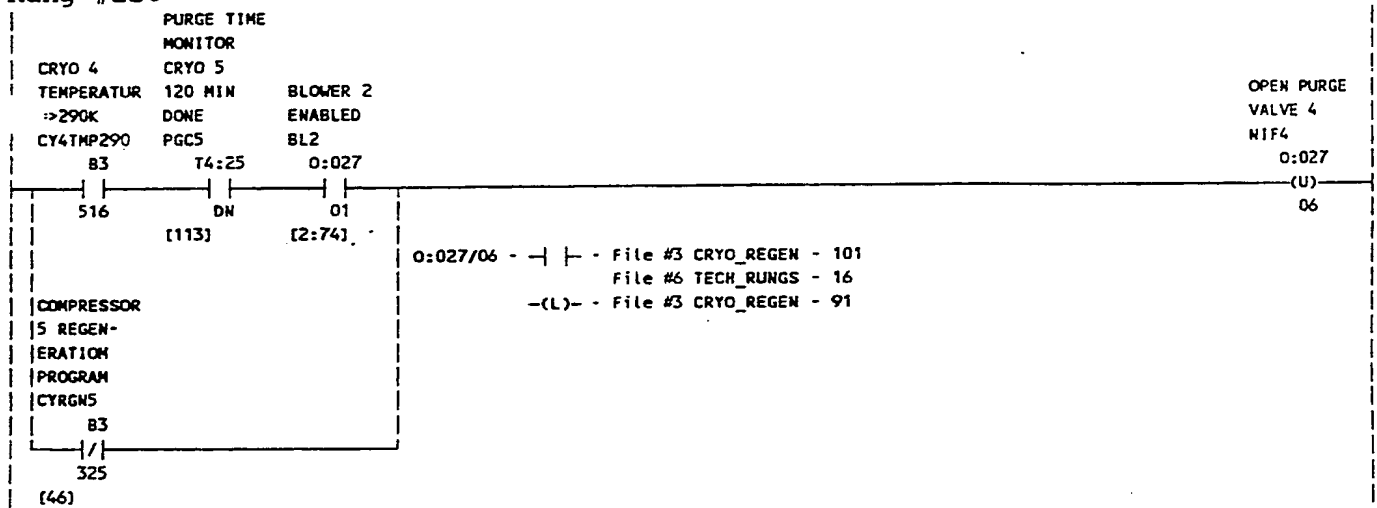


510

Rung #119

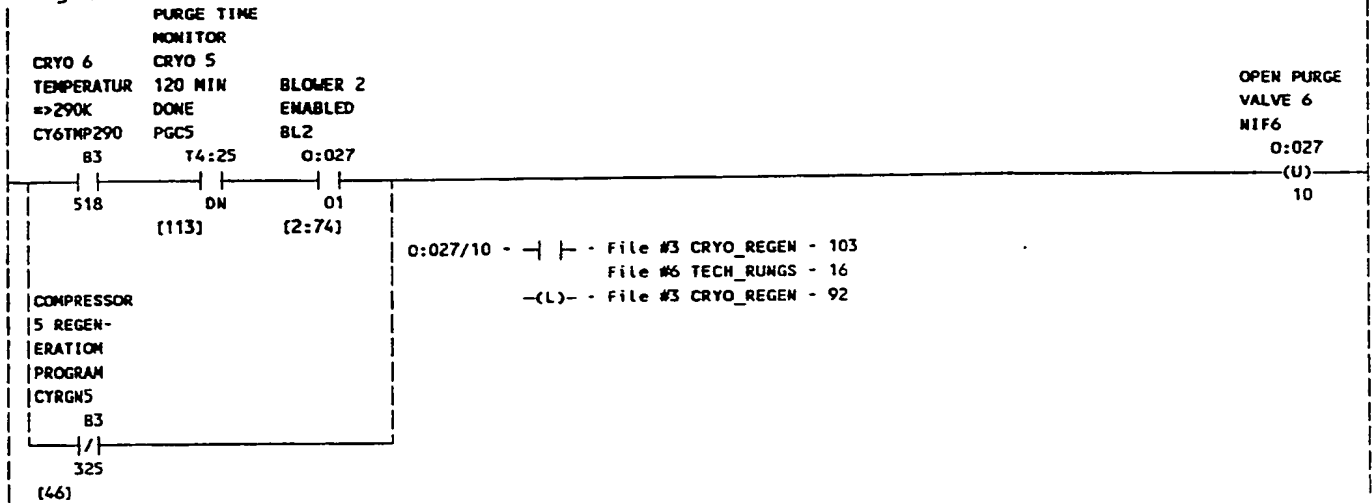


Rung #120

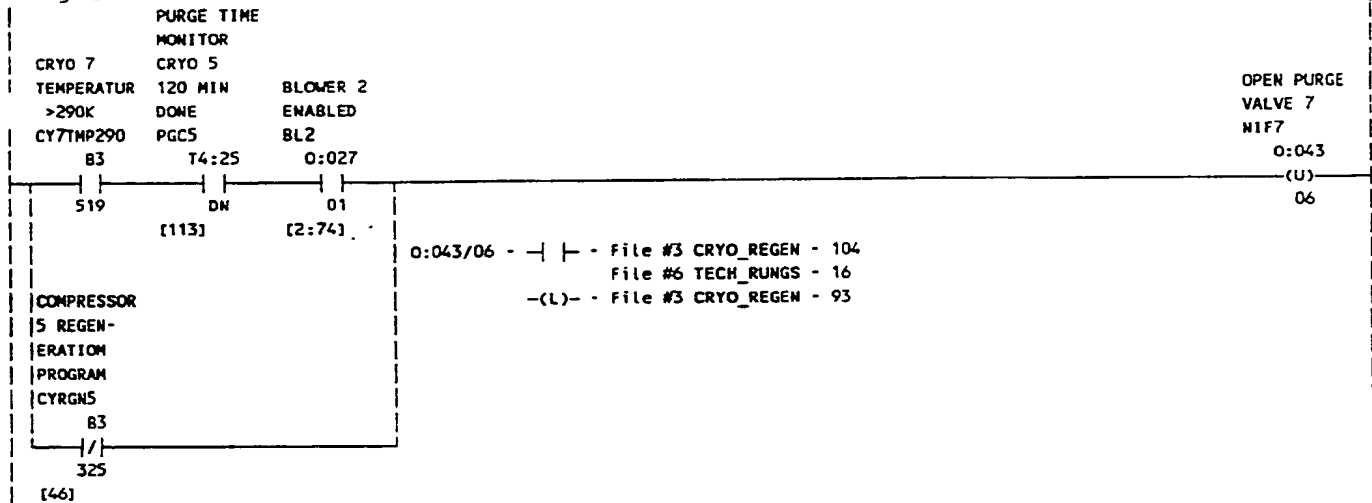


511

Rung #121

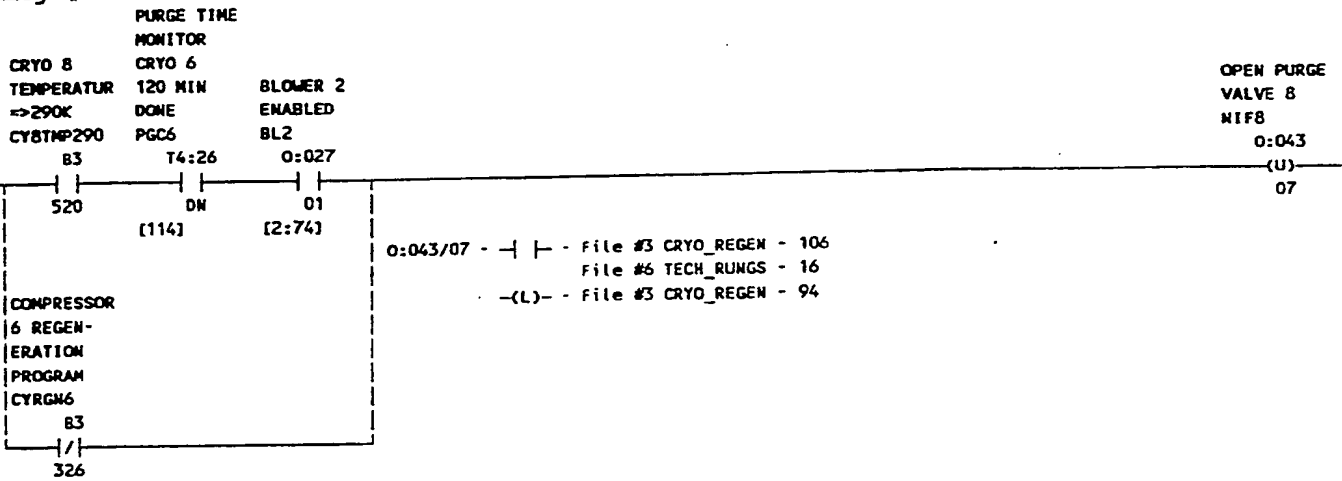


Rung #122

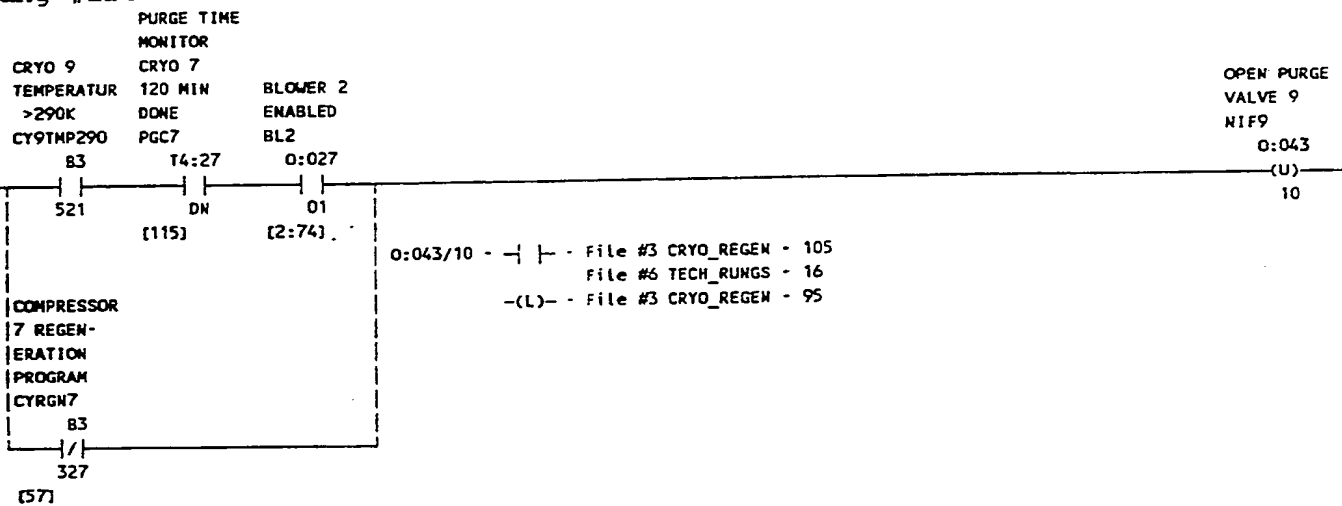


512

Rung #123

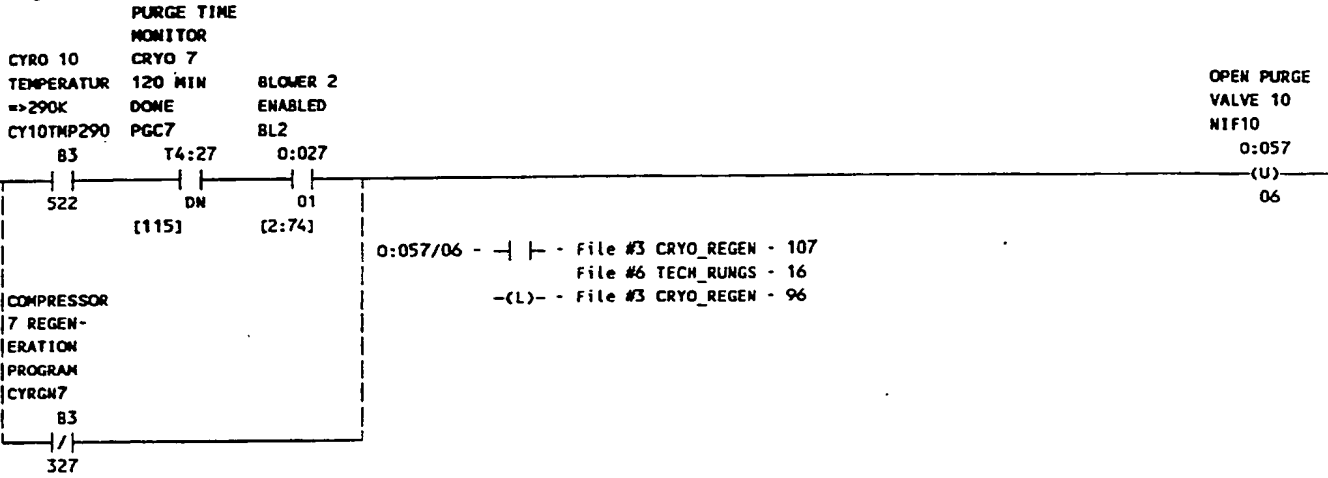


Rung #124

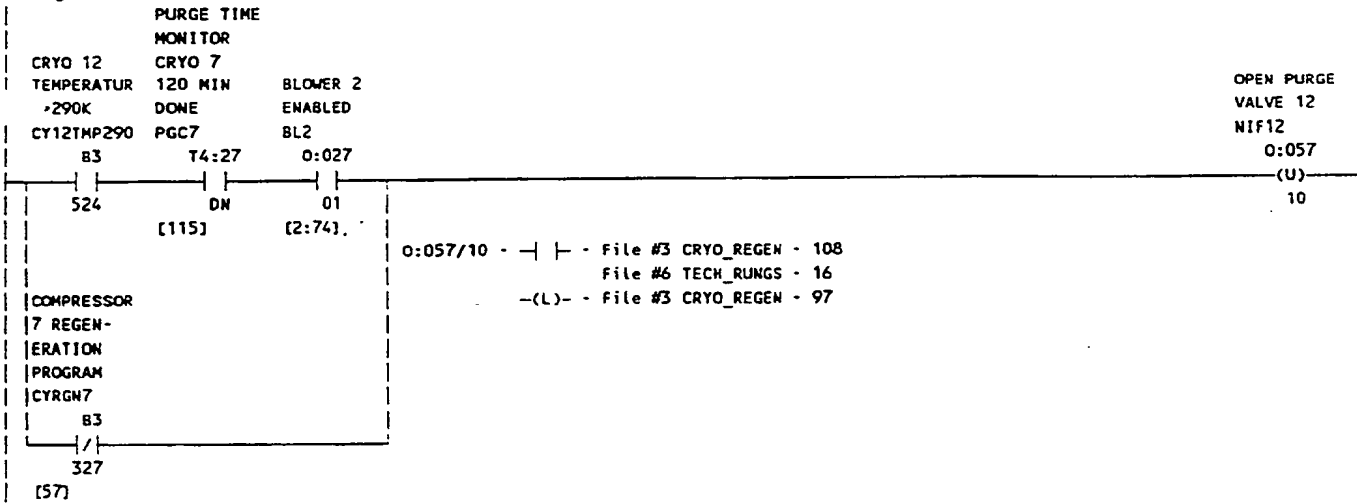


513

Rung #125

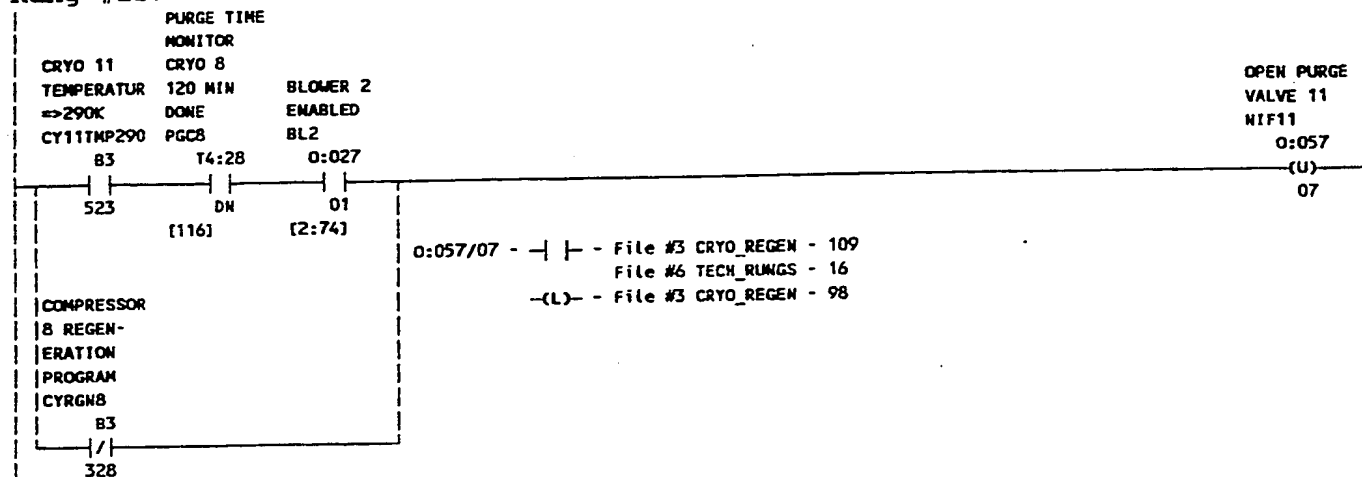


Rung #126

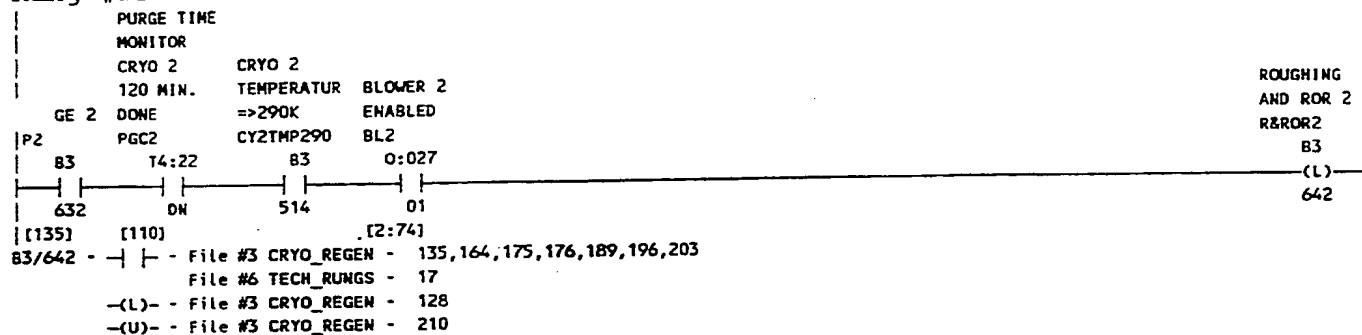


514

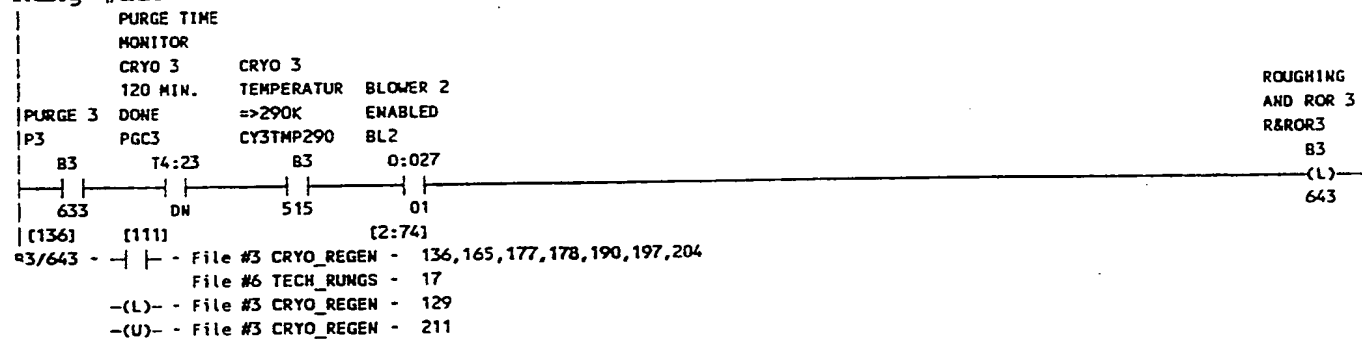
Rung #127



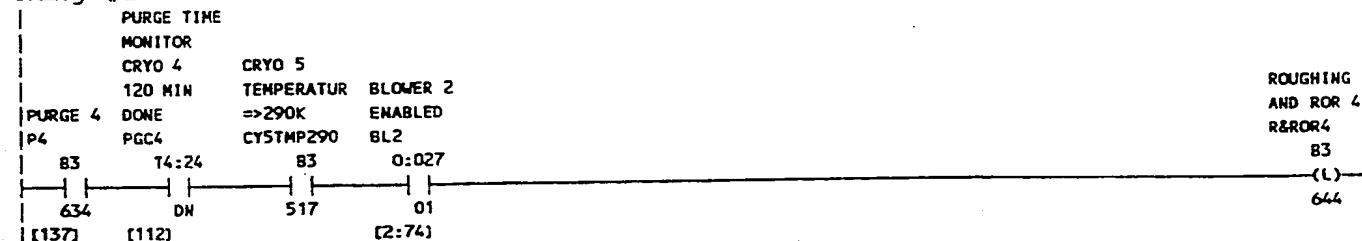
Rung #128



Rung #129



Rung #130



515

83/644 - | | - File #3 CRYO_REGEN - 137,166,179,180,191,198,205
 File #6 TECH_RUNGS - 17
 -(L)- File #3 CRYO_REGEN - 130
 -(U)- File #3 CRYO_REGEN - 212

Rung #131

PURGE TIME		MONITOR		CRYO 5	CRYO 4	CRYO 6	CRYO 7	BLOWER 2	ROUGHING AND ROR 5
PURGE 5	120 MIN	DONE	==>290K	==>290K	==>290K	==>290K	ENABLED		
P5	PGC5	CY4TMP290	CY6TMP290	CY7TMP290	BL2				
83	T4:25	83	83	83	0:027				
635	DN	516	518	519	01				
[138]	[113]				[2:74]				

83/645 - | | - File #3 CRYO_REGEN - 138,167,168,169,181,182,192,199,206
 File #6 TECH_RUNGS - 17
 -(L)- File #3 CRYO_REGEN - 131
 -(U)- File #3 CRYO_REGEN - 213

Rung #132

PURGE TIME		MONITOR		CRYO 6	CRYO 8	BLOWER 2	ROUGHING AND ROR 6
PURGE 6	120 MIN	DONE	==>290K	ENABLED			
P6	PGC6	CY8TMP290	BL2				
83	T4:26	83	0:027				
636	DN	520	01				
[139]	[114]		[2:74]				

83/646 - | | - File #3 CRYO_REGEN - 139,170,183,184,193,200,207
 File #6 TECH_RUNGS - 17
 -(L)- File #3 CRYO_REGEN - 132
 -(U)- File #3 CRYO_REGEN - 214

Rung #133

PURGE TIME		MONITOR		CRYO 7	CRYO 9	CRYO 10	CRYO 12	BLOWER 2	ROUGHING AND ROR 7
PURGE 7	120 MIN	DONE	==>290K	==>290K	==>290K	ENABLED			
P7	PGC7	CY9TMP290	CY10TMP290	CY12TMP290	BL2				
83	T4:27	83	83	83	0:027				
637	DN	521	522	524	01				
[140]	[115]				[2:74]				

83/647 - | | - File #3 CRYO_REGEN - 140,171,172,173,185,186,194,201,208
 File #6 TECH_RUNGS - 17
 -(L)- File #3 CRYO_REGEN - 133
 -(U)- File #3 CRYO_REGEN - 215

ung #134

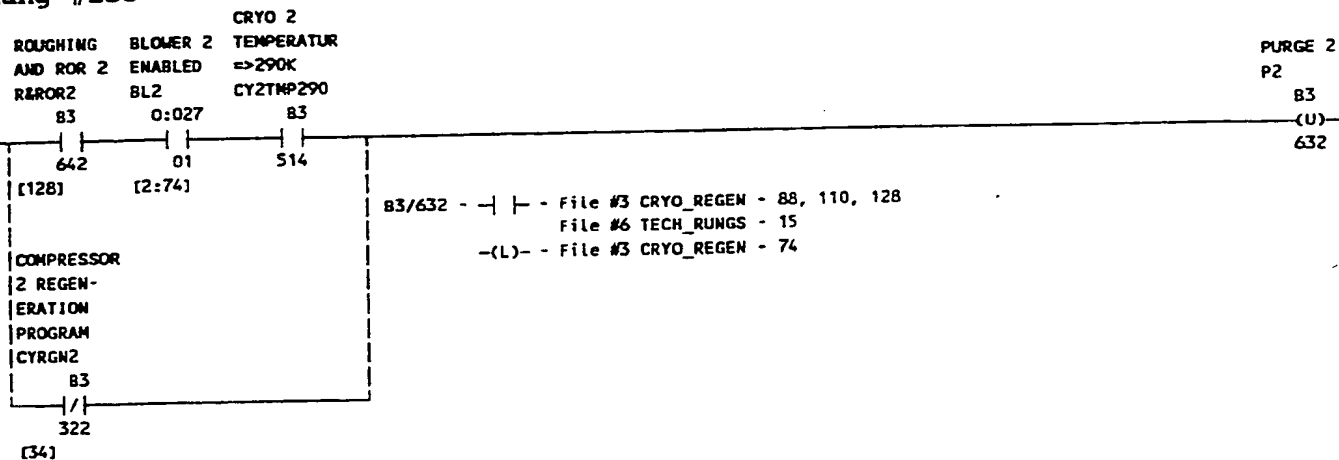
PURGE TIME		MONITOR		CRYO 8	CRYO 11	BLOWER 2	ROUGHING AND ROR 8
PURGE 8	120 MIN	DONE	==>290K	ENABLED			
P8	PGC8	CY11TMP290	BL2				
83	T4:28	83	0:027				
638	DN	523	01				
[141]	[116]		[2:74]				

83/648 - | | - File #3 CRYO_REGEN - 141,174,187,188,195,202,209
 File #6 TECH_RUNGS - 17

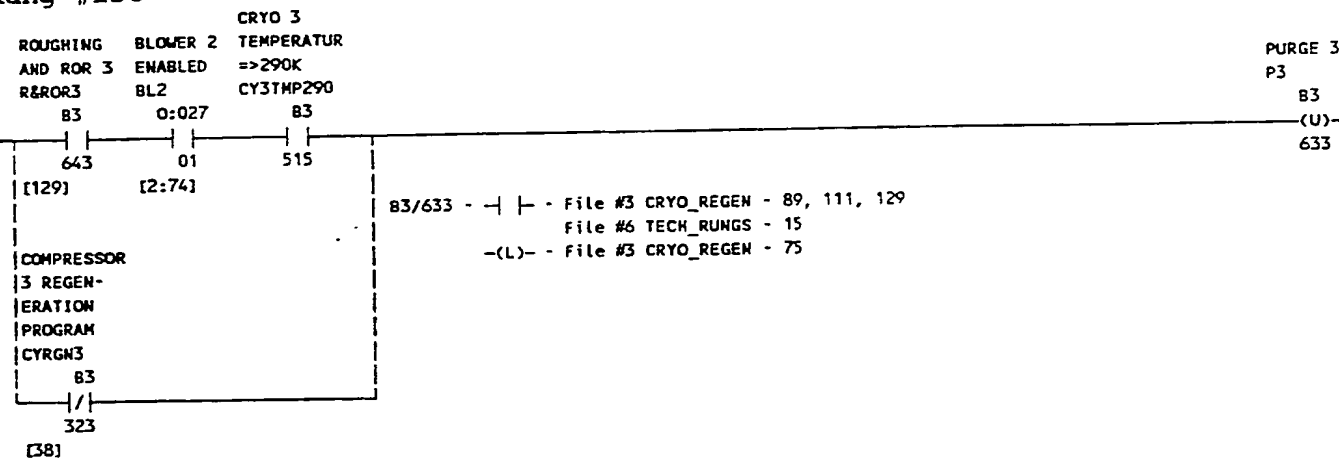
516

-(L)- - File #3 CRYO_REGEN - 134
 -(U)- - File #3 CRYO_REGEN - 216

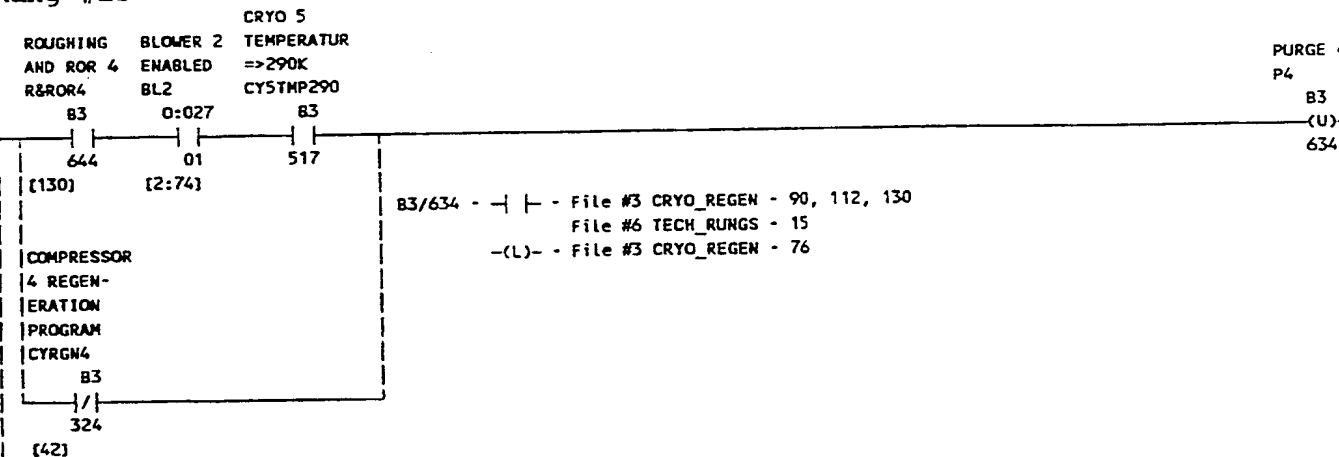
Rung #135



Rung #136

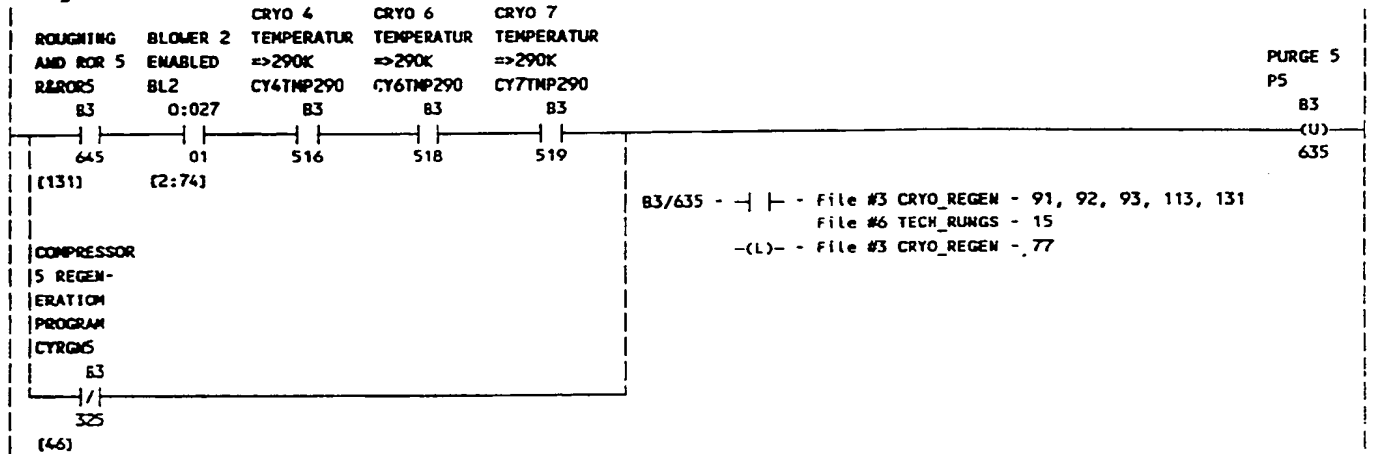


Rung #137

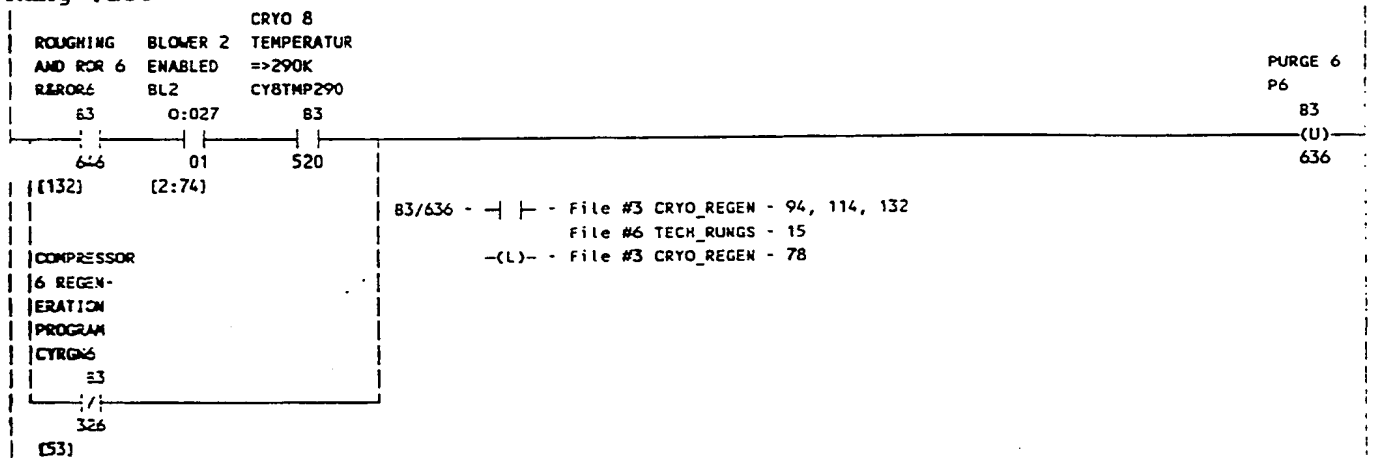


517

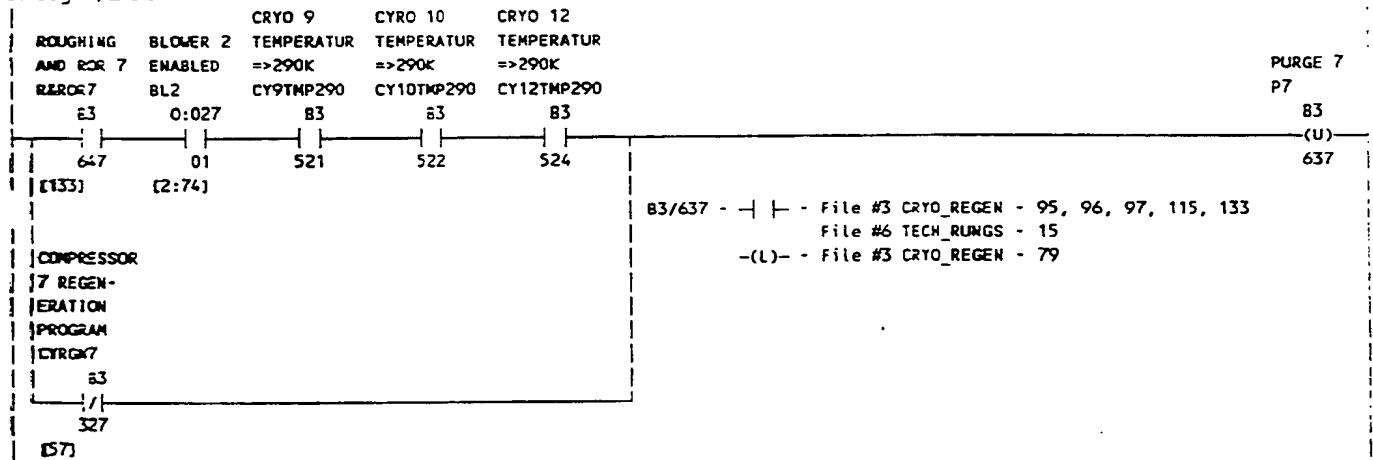
Rung #138



Rung #139

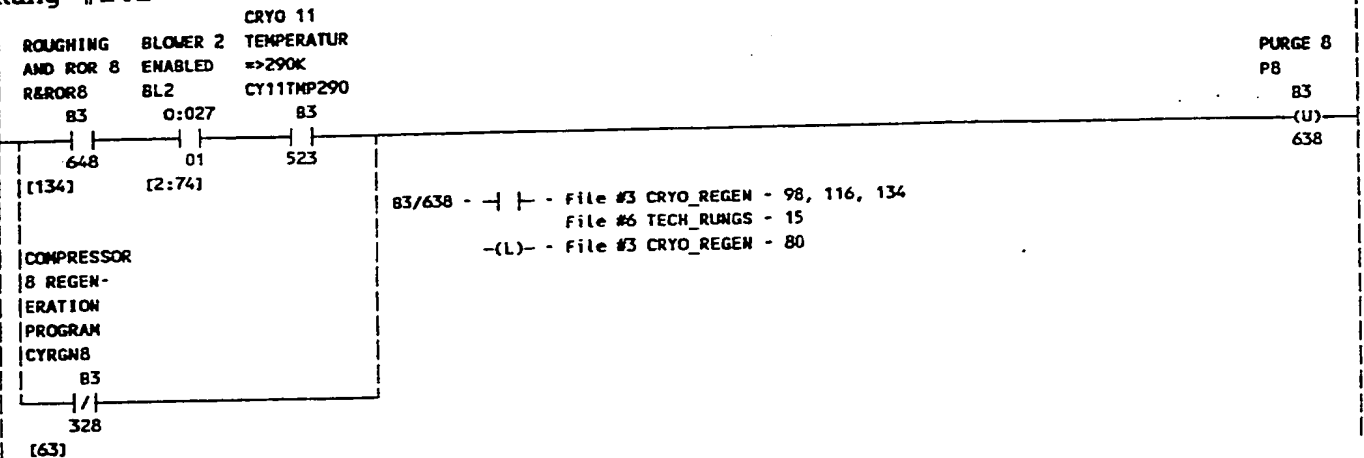


Rung #140

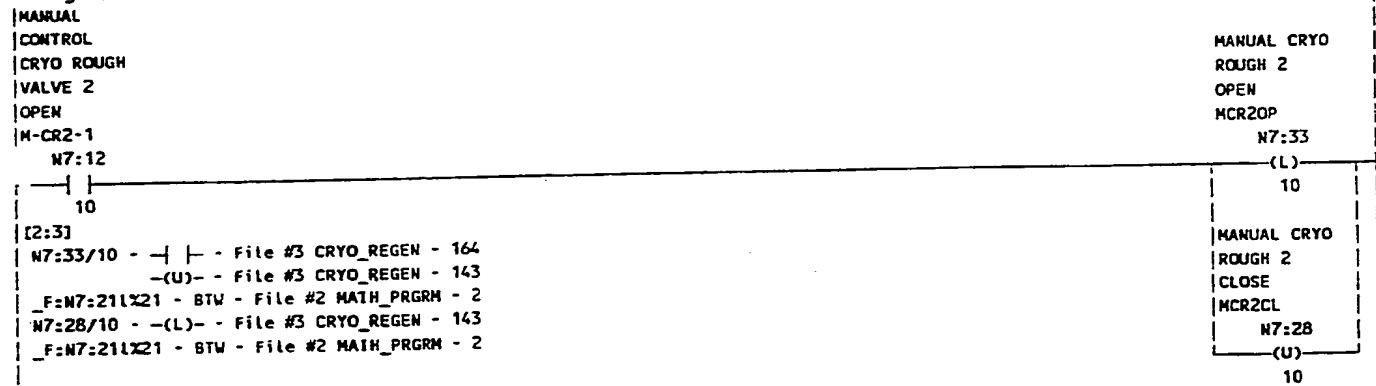


518

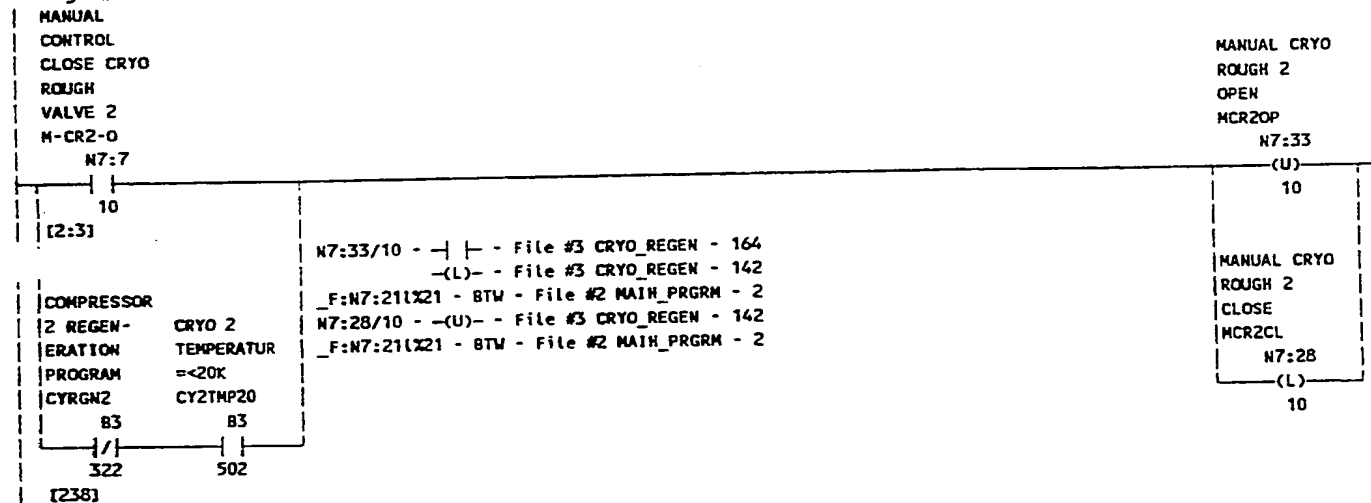
Rung #141



Rung #142



Rung #143



519

Rung #144

MANUAL
CONTROL
CRYO ROUGH
VALVE 3
OPEN
M-CR3-1

N7:12

11

(2:3)

N7:33/11 - | | - File #3 CRYO_REGEN - 165
-(U)- - File #3 CRYO_REGEN - 145
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/11 - -(L)- - File #3 CRYO_REGEN - 145
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 3
OPEN
MCR3OP
N7:33

(L)

11

MANUAL CRYO
ROUGH 3
CLOSE
MCR3CL
N7:28
(U)

11

Rung #145

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 3
M-CR3-0

N7:7

11

(2:3)

COMPRESSOR
3 REGEN- CRYO 3
ERATION TEMPERATUR
PROGRAM =<20K
CYRGMS CYSTMP20
83 83
323 503

N7:33/11 - | | - File #3 CRYO_REGEN - 165
-(L)- - File #3 CRYO_REGEN - 144
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/11 - -(U)- - File #3 CRYO_REGEN - 144
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 3
OPEN
MCR3OP
N7:33

(U)

11

MANUAL CRYO
ROUGH 3
CLOSE
MCR3CL
N7:28
(L)

11

(239)

Rung #146

MANUAL
CONTROL
CRYO ROUGH
VALVE 4
OPEN
M-CR4-1

N7:12

12

(2:3)

N7:33/12 - | | - File #3 CRYO_REGEN - 167
-(U)- - File #3 CRYO_REGEN - 147
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/12 - -(L)- - File #3 CRYO_REGEN - 147
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 4
OPEN
MCR4OP
N7:33

(L)

12

MANUAL CRYO
ROUGH 4
CLOSE
MCR4CL
N7:28
(U)

12

520

Rung #147

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 4
M-CR4-O

N7:7

MANUAL CRYO
ROUGH 4
OPEN
MCR4OP

N7:33

(U)

12

[2:3]

N7:33/12 - | | - File #3 CRYO_REGEN - 167
-(L)- - File #3 CRYO_REGEN - 146
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/12 - -(U)- - File #3 CRYO_REGEN - 146
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

COMPRESSOR

5 REGEN- CRYO 4
ERATION TEMPERATUR
PROGRAM =<20K
CYRGN5 CY4TMP20

B3

B3

325

504

MANUAL CRYO
ROUGH 4
CLOSE
MCR4CL

N7:28

(L)

12

[241]

Rung #148

MANUAL
CONTROL
CRYO ROUGH
OPEN
M-CR5-1

N7:12

MANUAL CRYO
ROUGH 5
OPEN
MCR5OP

N7:33

(L)

13

[2:3]

N7:33/13 - | | - File #3 CRYO_REGEN - 166
-(U)- - File #3 CRYO_REGEN - 149
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/13 - -(L)- - File #3 CRYO_REGEN - 149
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 5
CLOSE
MCR5CL

N7:28

(U)

13

Rung #149

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 5
M-CR5-O

N7:7

MANUAL CRYO
ROUGH 5
OPEN
MCR5OP

N7:33

(U)

13

[2:3]

N7:33/13 - | | - File #3 CRYO_REGEN - 166
-(L)- - File #3 CRYO_REGEN - 148
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/13 - -(U)- - File #3 CRYO_REGEN - 148
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

COMPRESSOR

4 REGEN- CRYO 5
ERATION TEMPERATUR
PROGRAM =<20K
CYRGN4 CY5TMP20

B3

B3

324

505

MANUAL CRYO
ROUGH 5
CLOSE
MCR5CL

N7:28

(L)

13

[240]

521

Rung #150

MANUAL
CONTROL
CRYO ROUGH
VALVE 6
OPEN
M-CR6-1

N7:12

14

[2:3]

N7:33/14 - | | - File #3 CRYO_REGEN - 168
-(U)- - File #3 CRYO_REGEN - 151
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/14 - -(L)- - File #3 CRYO_REGEN - 151
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 6
OPEN
MCR6OP

N7:33

-(L)-

14

MANUAL CRYO
ROUGH 6
CLOSE
MCR6CL

N7:28

-(U)-

14

Rung #151

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 6
M-CR6-0

N7:7

14

[2:3]

COMPRESSOR
S REGEN- CRYO 6
ERATION TEMPERATUR
PROGRAM =<20K
CYRGNS CY6TMP20
83 83
325 506

N7:33/14 - | | - File #3 CRYO_REGEN - 168
-(L)- - File #3 CRYO_REGEN - 150
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/14 - -(U)- - File #3 CRYO_REGEN - 150
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 6
OPEN
MCR6OP

N7:33

-(U)-

14

MANUAL CRYO
ROUGH 6
CLOSE
MCR6CL

N7:28

-(L)-

14

[241]

Rung #152

MANUAL
CONTROL
CRYO ROUGH
VALVE 7
OPEN
M-CR7-1

N7:12

15

[2:3]

N7:33/15 - | | - File #3 CRYO_REGEN - 169
-(U)- - File #3 CRYO_REGEN - 153
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/15 - -(L)- - File #3 CRYO_REGEN - 153
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 7
OPEN
MCR7OP

N7:33

-(L)-

15

MANUAL CRYO
ROUGH 7
CLOSE
MCR7CL

N7:28

-(U)-

15

522

Rung #153

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 7
M-CR7-0

N7:7

15
[2:3]

COMPRESSOR
5 REGEN- CRYO 7
ERATION TEMPERATUR
PROGRAM =<20K
CYRGMS CY7TMP20
83 83
325 507

N7:33/15 - | | - File #3 CRYO_REGEN - 169
-(L)- - File #3 CRYO_REGEN - 152
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:28/15 - -(U)- - File #3 CRYO_REGEN - 152
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 7
OPEN
MCR7OP

N7:33

(U)

15

MANUAL CRYO
ROUGH 7
CLOSE
MCR7CL
N7:28
(L)
15

[241]

Rung #154

MANUAL
CONTROL
CRYO ROUGH
VALVE 8
PEN

M-CR8-1

N7:13

0

[2:3]

N7:34/0 - | | - File #3 CRYO_REGEN - 170
-(U)- - File #3 CRYO_REGEN - 155
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/0 - -(L)- - File #3 CRYO_REGEN - 155
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 8
OPEN
MCR8OP

N7:34

(L)

0

MANUAL CRYO
ROUGH 8
CLOSE
MCR8CL
N7:29
(U)
0

Rung #155

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 8
M-CR8-0

N7:8

0

[2:3]

COMPRESSOR
6 REGEN- CRYO 8
ERATION TEMPERATUR
PROGRAM =<20K
CYRGMS CY8TMP20
83 83
326 508

N7:34/0 - | | - File #3 CRYO_REGEN - 170
-(L)- - File #3 CRYO_REGEN - 154
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/0 - -(U)- - File #3 CRYO_REGEN - 154
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 8
OPEN
MCR8OP

N7:34

(U)

0

MANUAL CRYO
ROUGH 8
CLOSE
MCR8CL
N7:29
(L)
0

[242]

523

Rung #156

MANUAL
CONTROL
CRYO ROUGH
VALVE 9
OPEN
M-CR9-1

N7:13

MANUAL CRYO
ROUGH 9
OPEN
MCR9OP

N7:34

(L)

1

[2:3]

N7:34/1 - | | - File #3 CRYO_REGEN - 171
-(U)- - File #3 CRYO_REGEN - 157
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/1 - -(L)- - File #3 CRYO_REGEN - 157
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

N7:29

(U)

1

Rung #157

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 9
M-CR9-0

N7:8

MANUAL CRYO
ROUGH 9
OPEN
MCR9OP

N7:34

(U)

1

[2:3]

COMPRESSOR
7 REGEN- CRYO 9
ERATION TEMPERATUR
PROGRAM =<20K
CYRGN7 CY9TMP20
B3 83
327 509

N7:34/1 - | | - File #3 CRYO_REGEN - 171
-(L)- - File #3 CRYO_REGEN - 156
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/1 - -(U)- - File #3 CRYO_REGEN - 156
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

N7:29

(L)

1

(243)

Rung #158

MANUAL
CONTROL
CRYO ROUGE
VALVE 10
OPEN
M-CR10-1

N7:13

MANUAL CRYO
ROUGH 10
OPEN
MCR10OP

N7:34

(L)

2

[2:3]

N7:34/2 - | | - File #3 CRYO_REGEN - 172
-(U)- - File #3 CRYO_REGEN - 159
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/2 - -(L)- - File #3 CRYO_REGEN - 159
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

N7:29

(U)

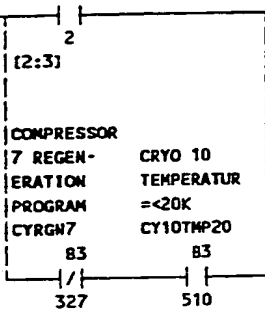
2

524

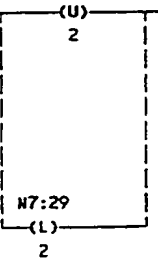
Rung #159

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 10
M-CR10-O
N7:8

MANUAL CRYO
ROUGH 10
OPEN
MCR10OP
N7:34



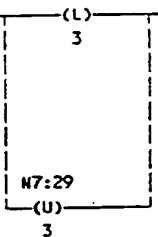
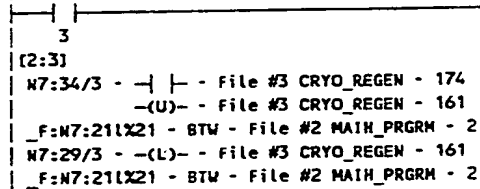
N7:34/2 - | | - File #3 CRYO_REGEN - 172
-(L)- - File #3 CRYO_REGEN - 158
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/2 - -(U)- - File #3 CRYO_REGEN - 158
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2



Rung #160

MANUAL
CONTROL
CRYO 11
OPEN
CR11-1
N7:13

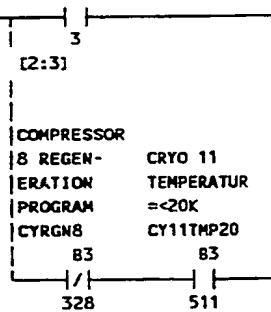
MANUAL CRYO
ROUGH 11
OPEN
MCR11OP
N7:34



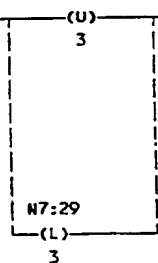
Rung #161

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 11
M-CR11-O
N7:8

MANUAL CRYO
ROUGH 11
OPEN
MCR11OP
N7:34



N7:34/3 - | | - File #3 CRYO_REGEN - 174
-(L)- - File #3 CRYO_REGEN - 160
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/3 - -(U)- - File #3 CRYO_REGEN - 160
_F:N7:21(X21 - BTW - File #2 MAIN_PRGRM - 2



(244)

525

Rung #162

MANUAL
CONTROL
CRYO ROUGH
VALVE 12
OPEN
M-CR12-1

N7:13

4

[2:3]

N7:34/4 - | | - File #3 CRYO_REGEN - 173
-(U)- - File #3 CRYO_REGEN - 163
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/4 - -(L)- - File #3 CRYO_REGEN - 163
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 12
OPEN
MCR120P

N7:34

(L)

4

N7:29

(U)

4

Rung #163

MANUAL
CONTROL
CLOSE CRYO
ROUGH
VALVE 12
M-RV12-0

N7:8

4

[2:3]

COMPRESSOR

7 REGEN- CRYO 12

ERATION TEMPERATUR

PROGRAM =<20K

CYRGW7 CY12TMP20

83

83

327

512

[243]

N7:34/4 - | | - File #3 CRYO_REGEN - 173
-(L)- - File #3 CRYO_REGEN - 162
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2
N7:29/4 - -(U)- - File #3 CRYO_REGEN - 162
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

MANUAL CRYO
ROUGH 12
OPEN
MCR120P

N7:34

(U)

4

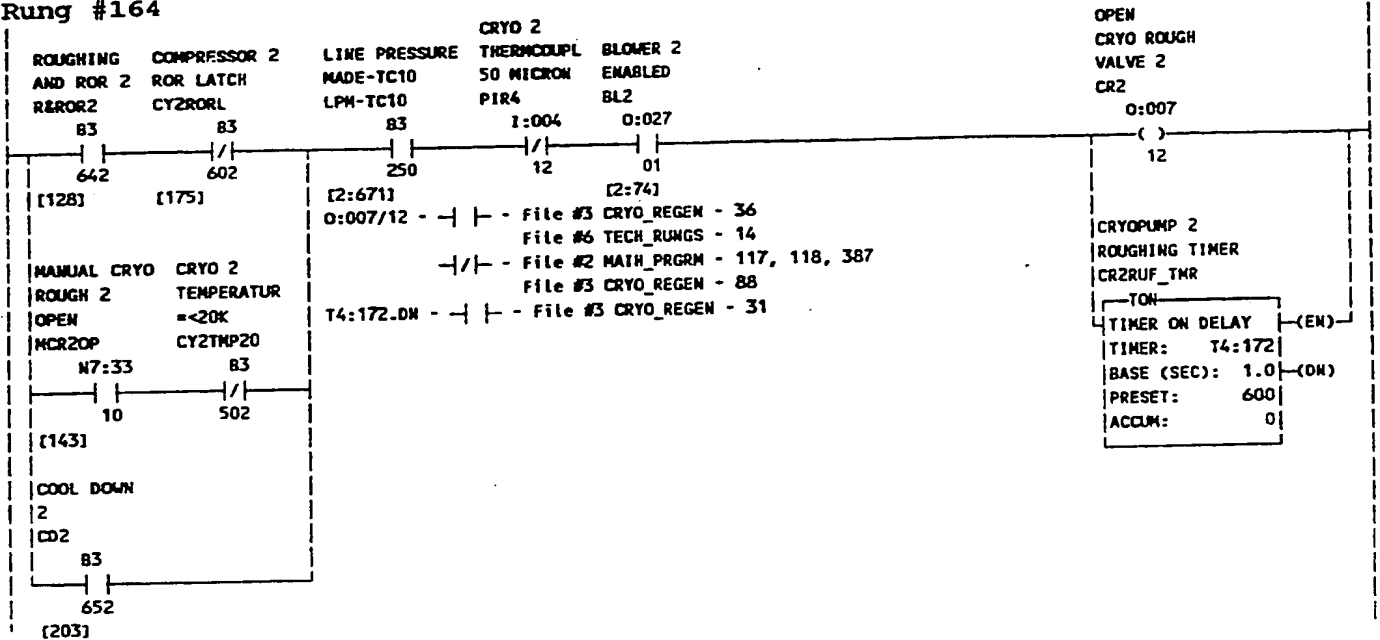
N7:29

(L)

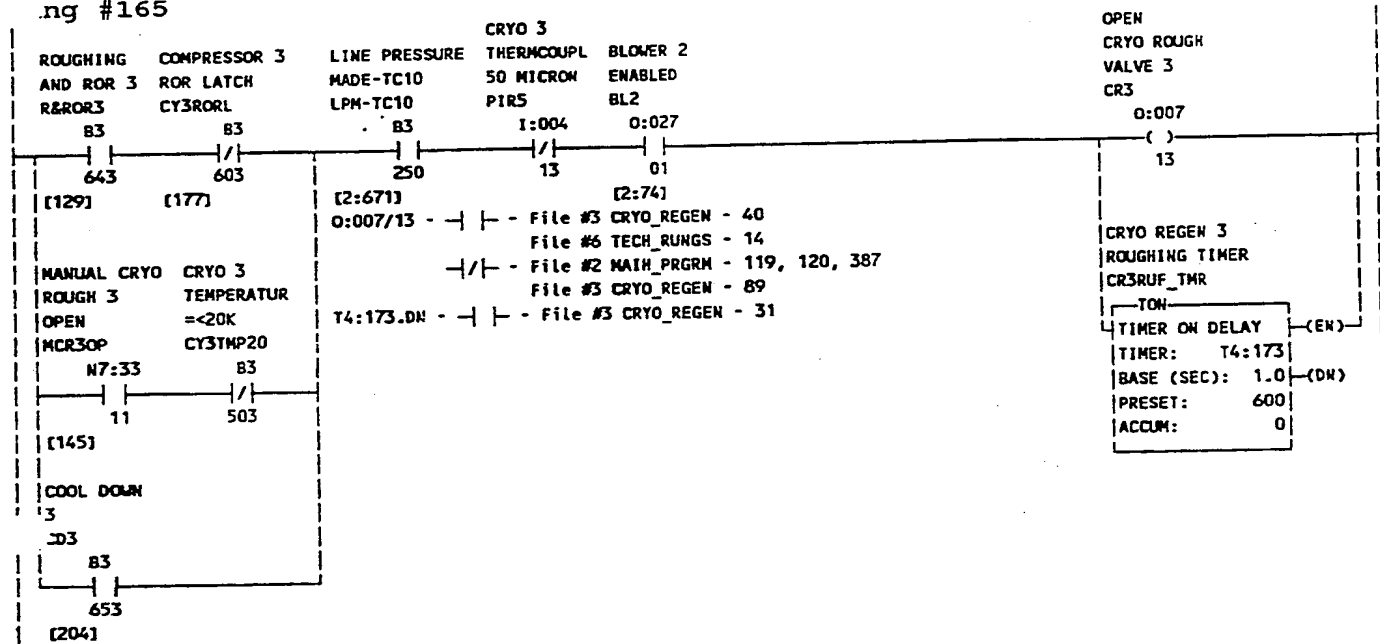
4

526

Rung #164

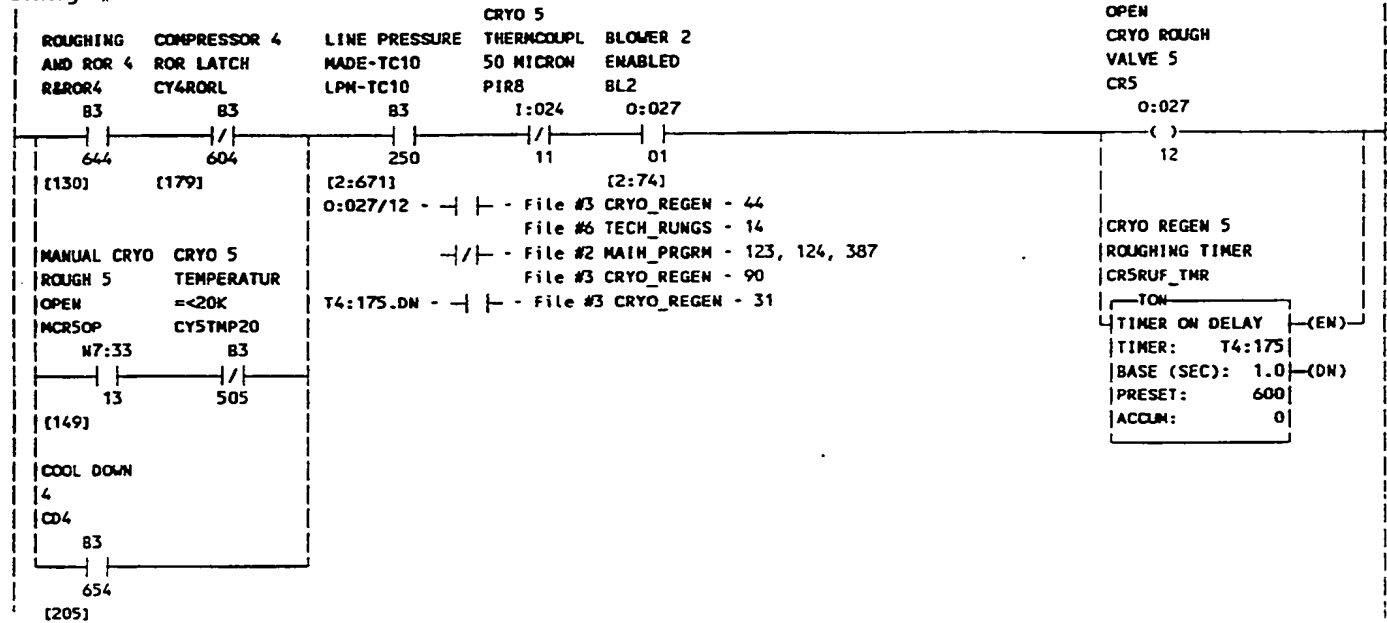


ng #165

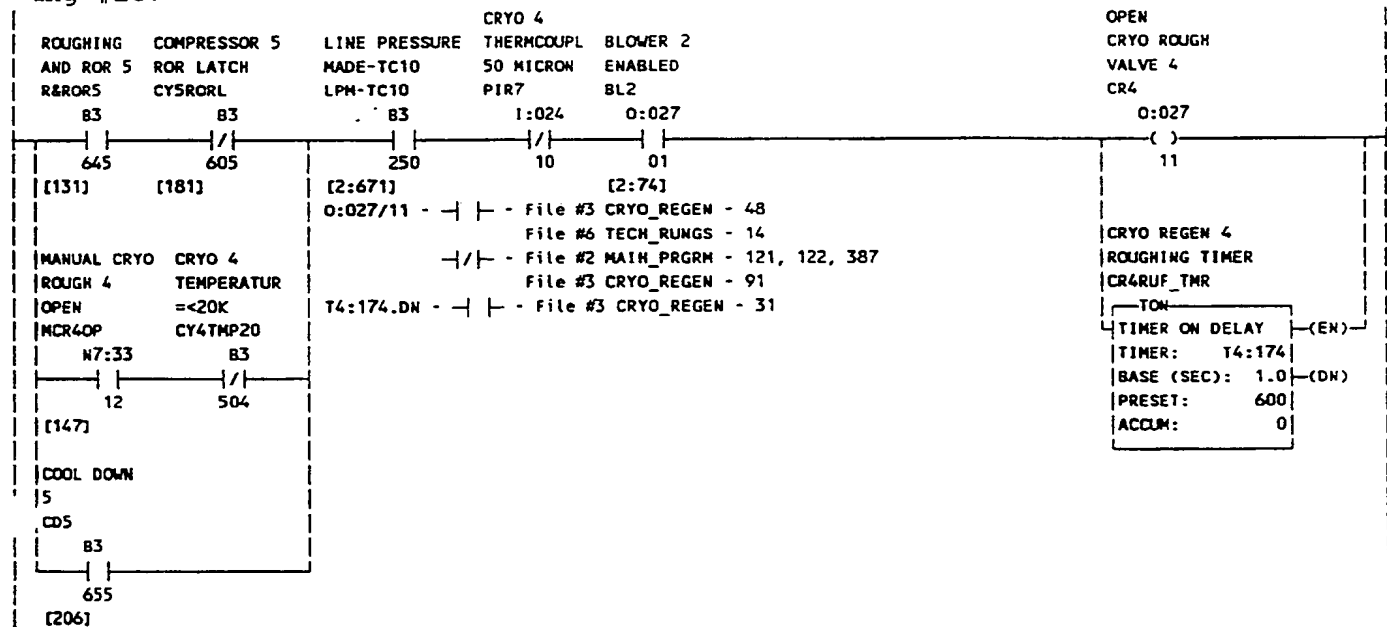


527

Rung #166

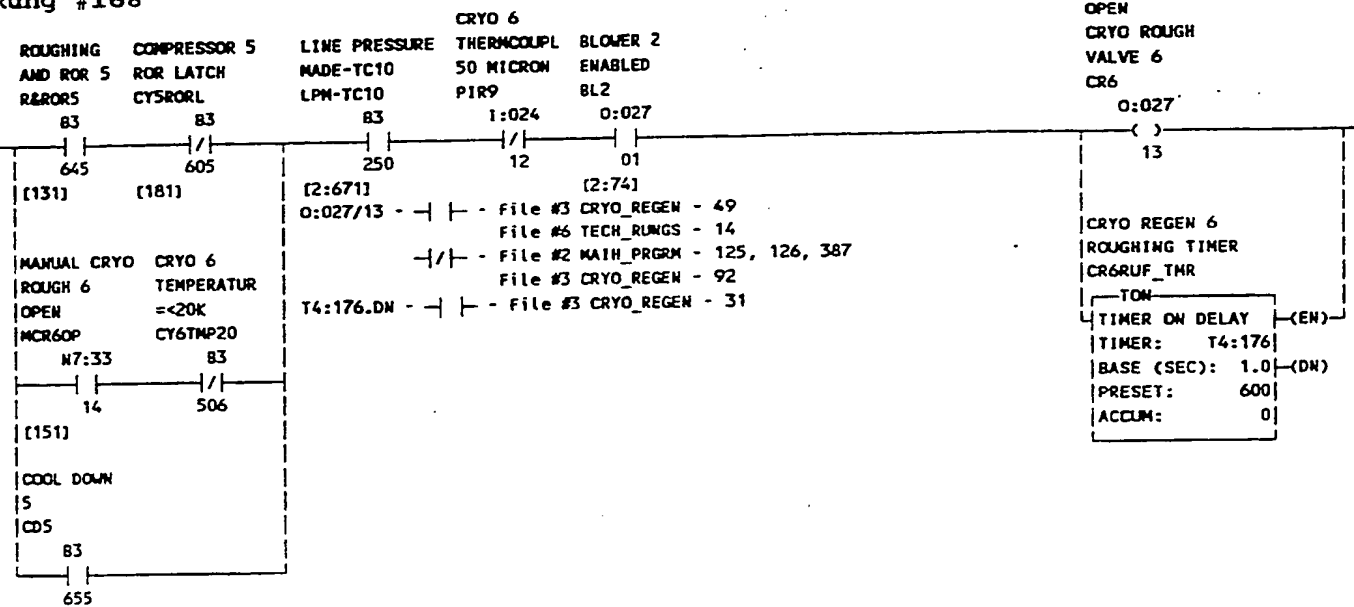


Rung #167

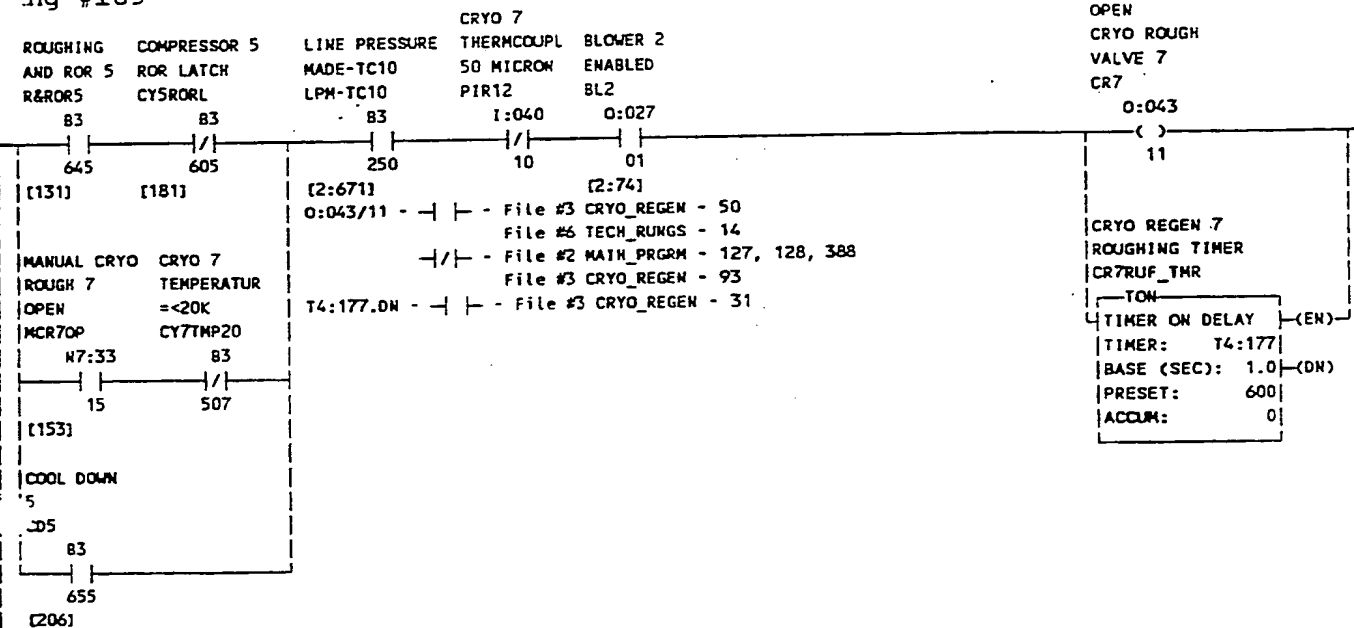


528

Rung #168

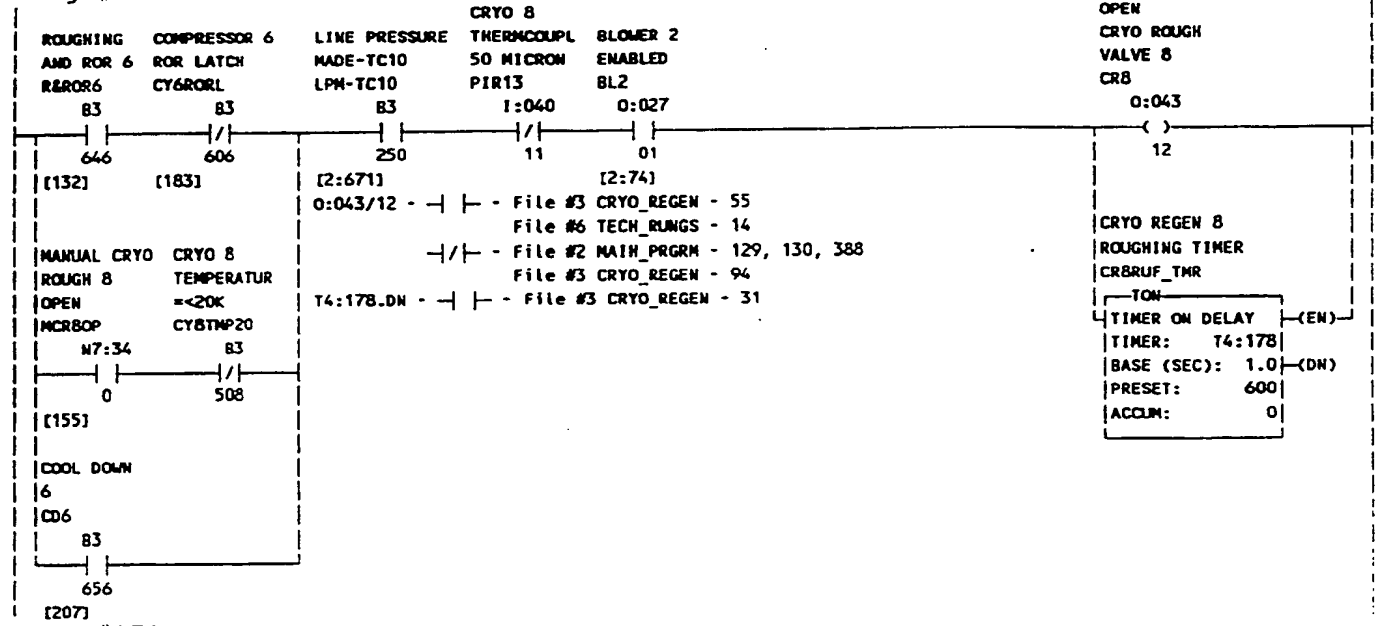


ng #169

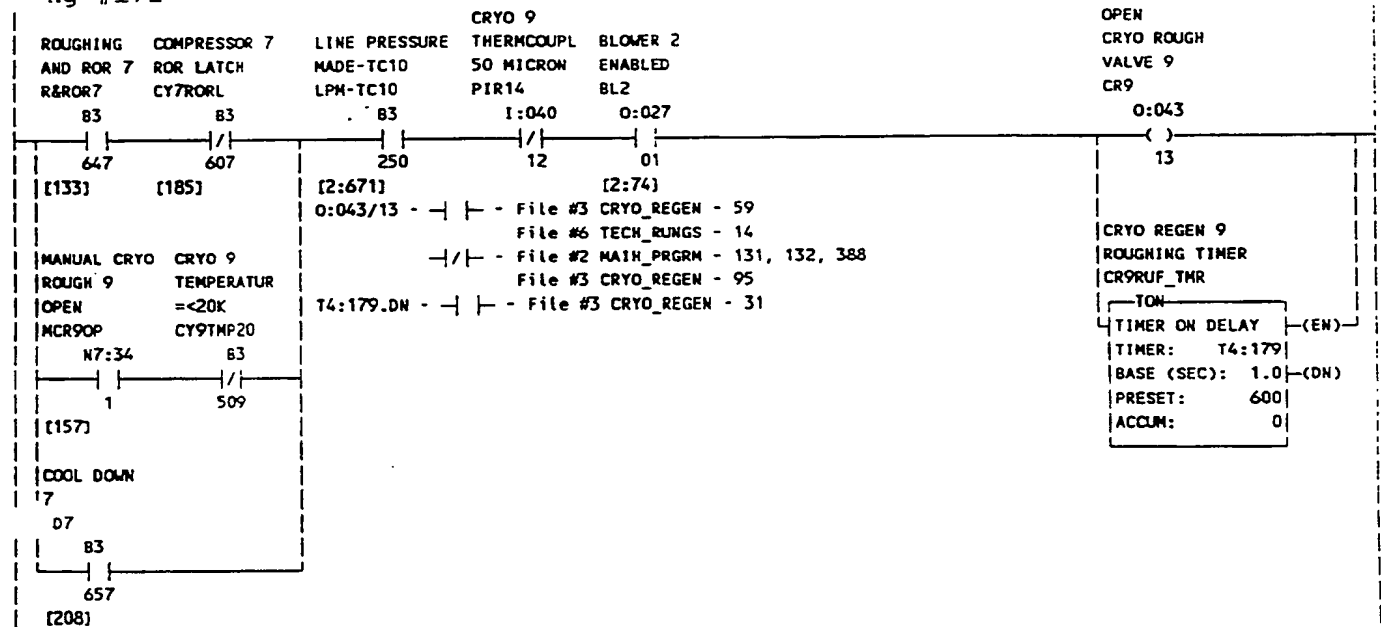


529

Rung #170

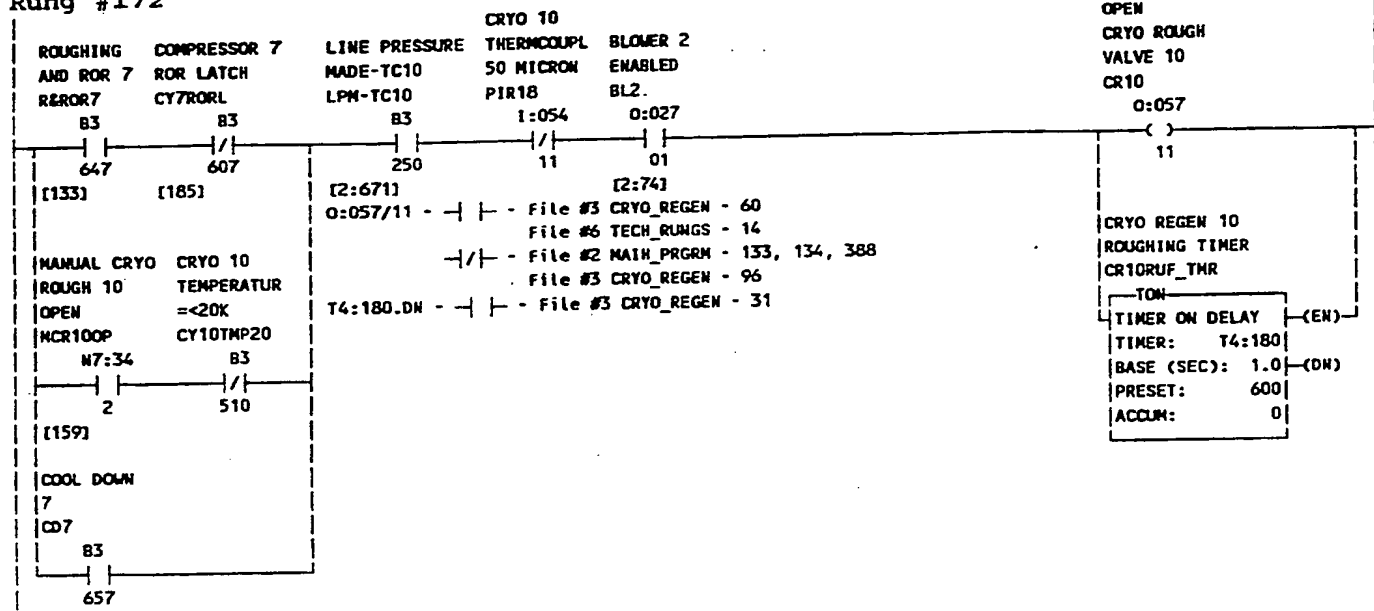


Rung #171

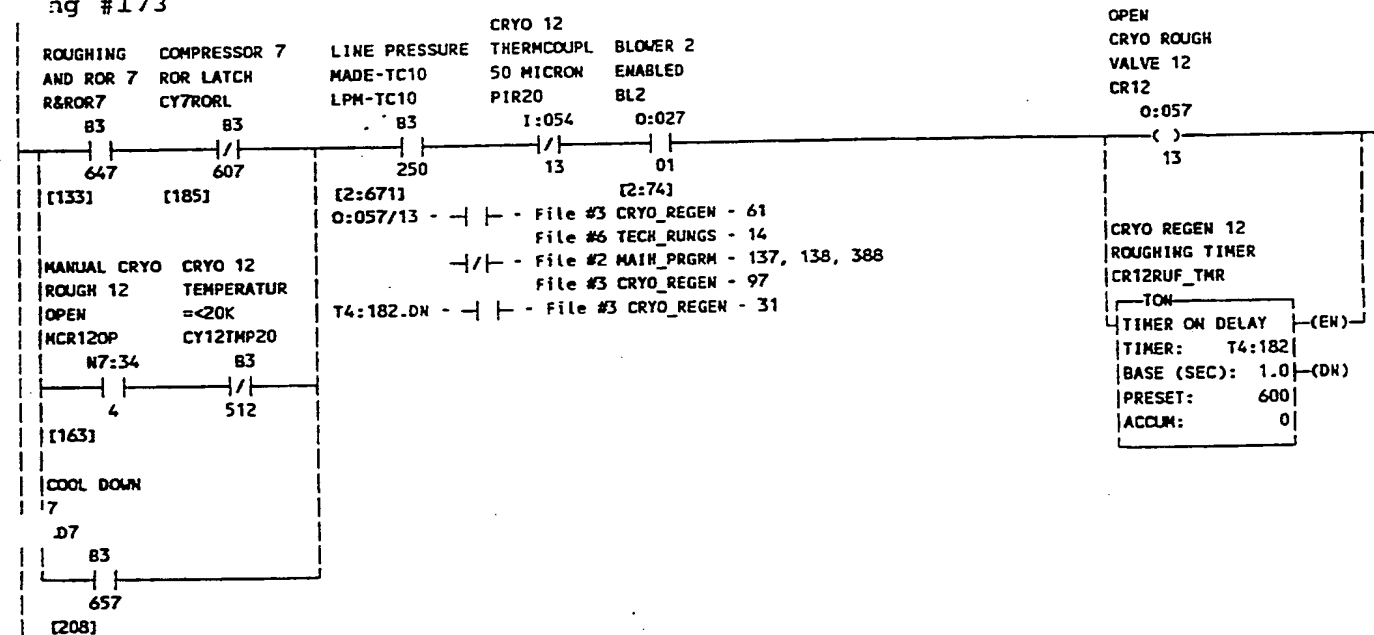


530

Rung #172

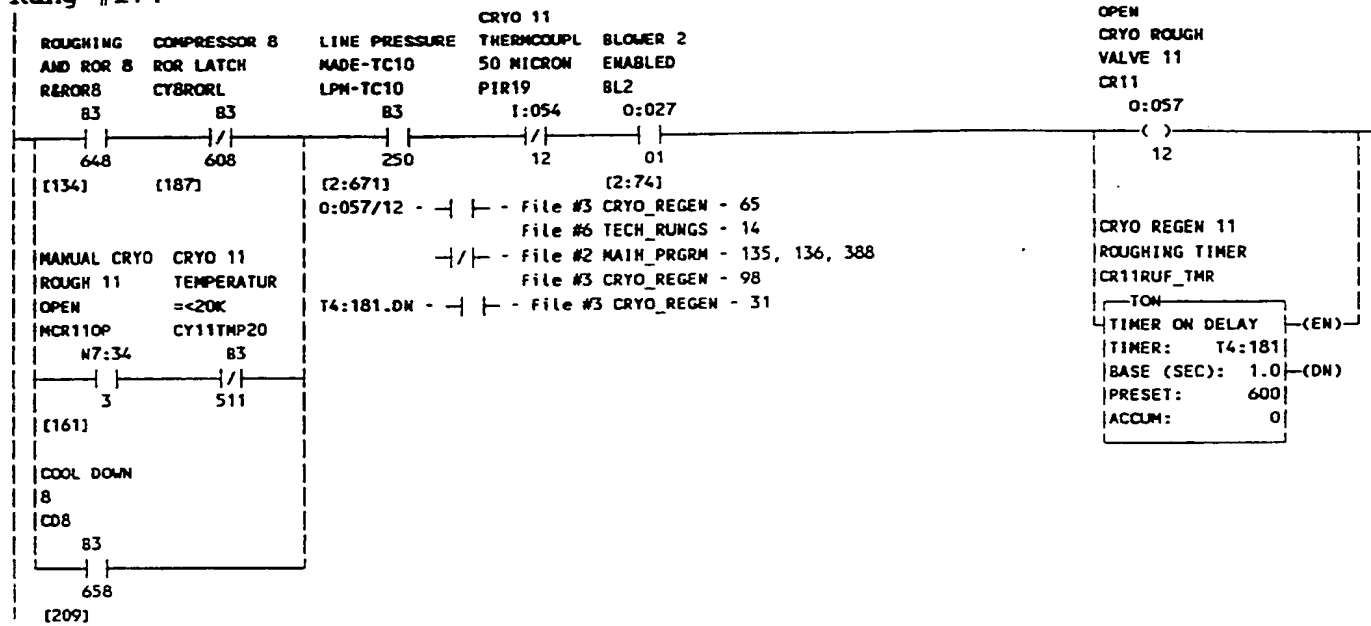


Rung #173

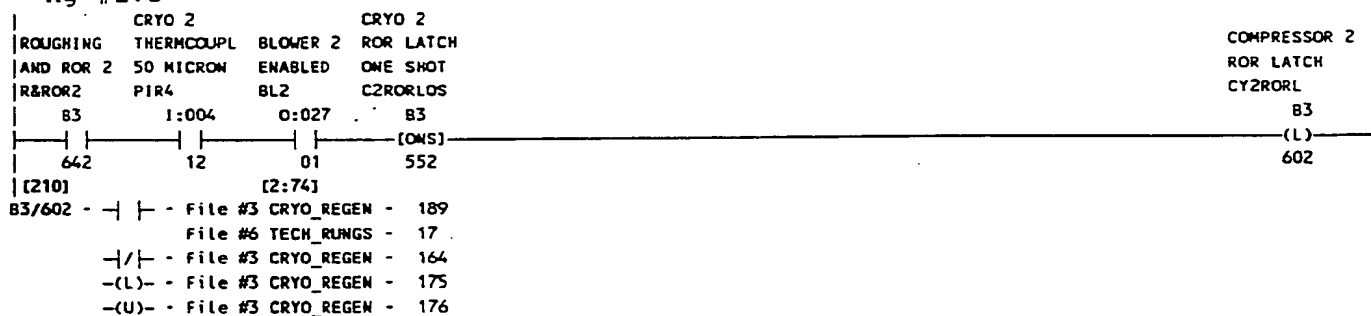


531

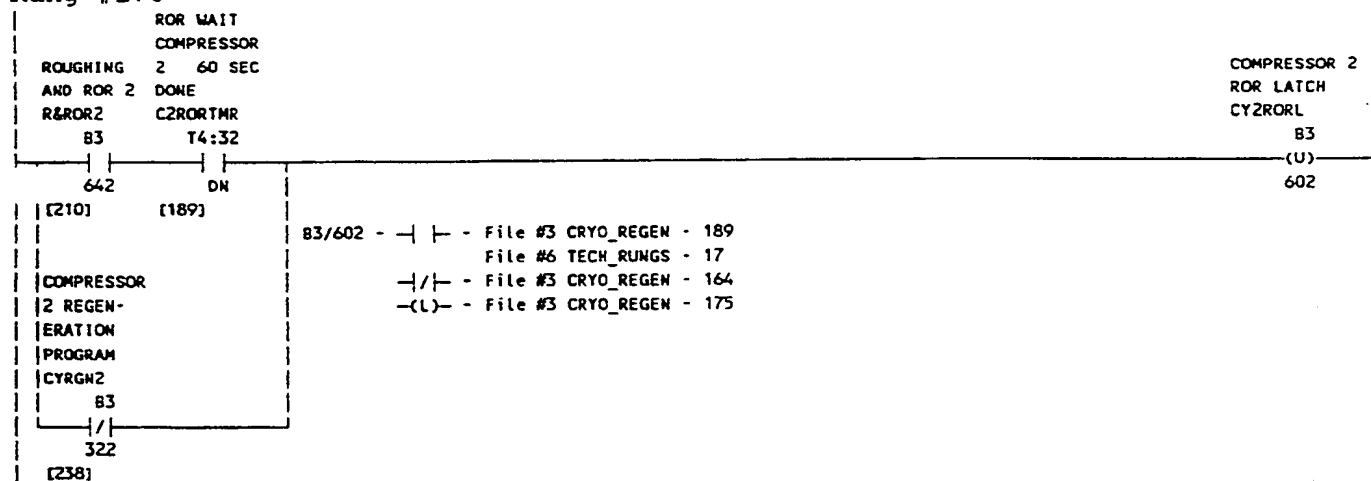
Rung #174



Rung #175

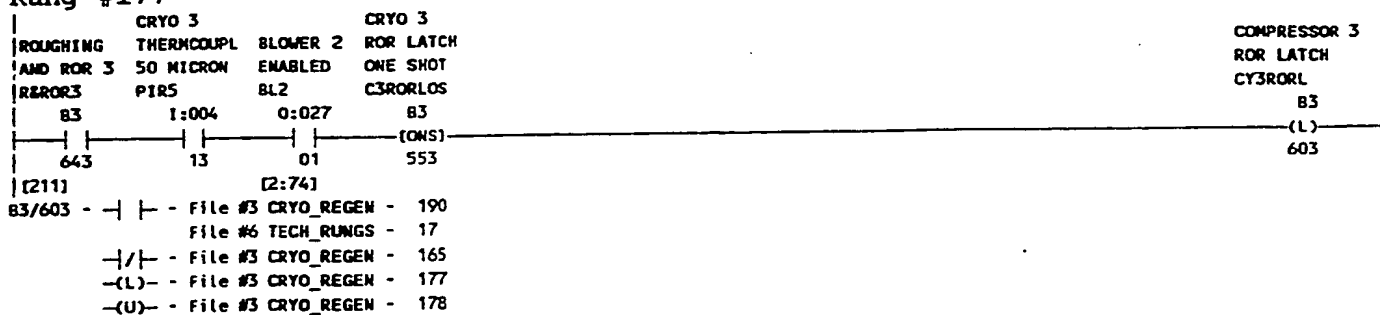


Rung #176

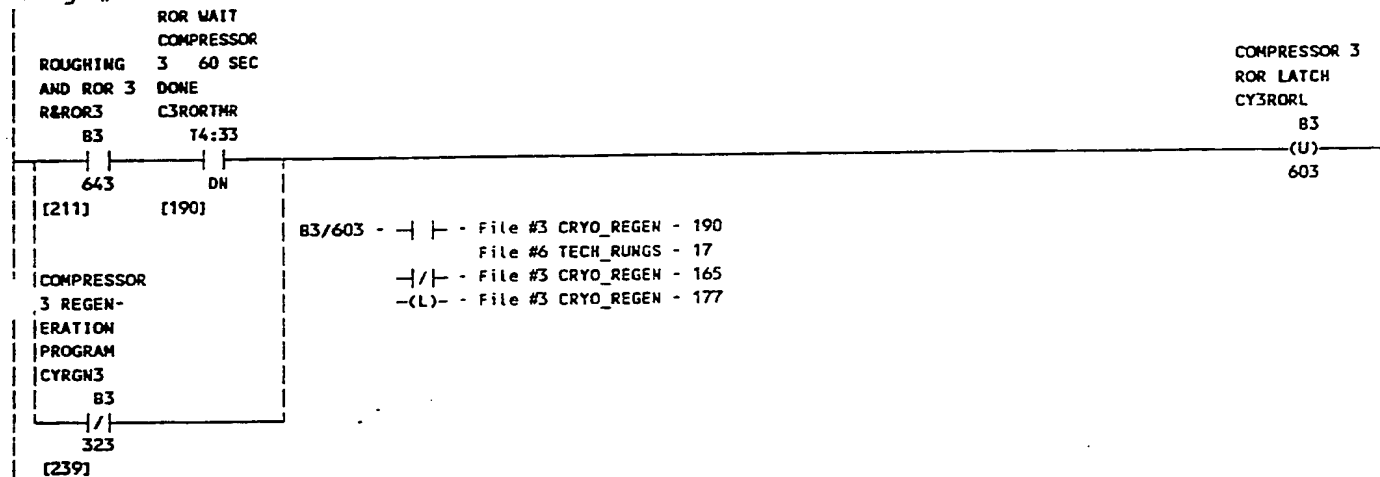


532

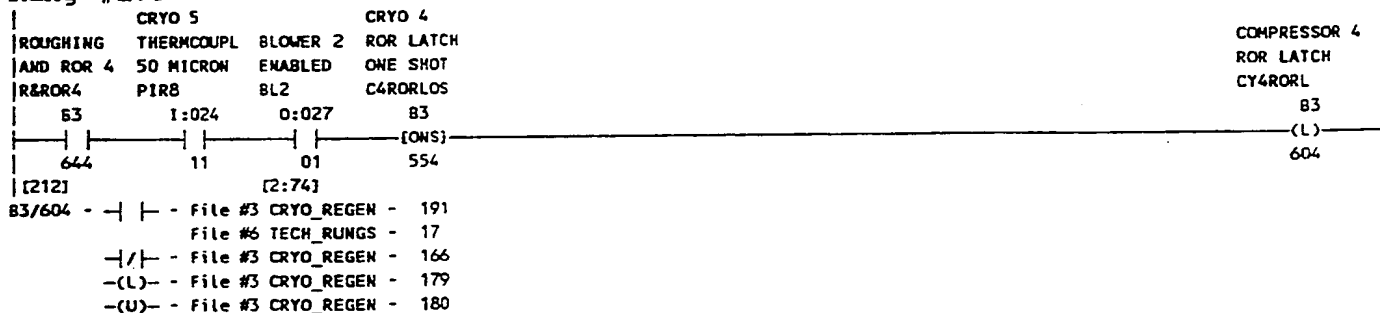
Rung #177



Rung #178

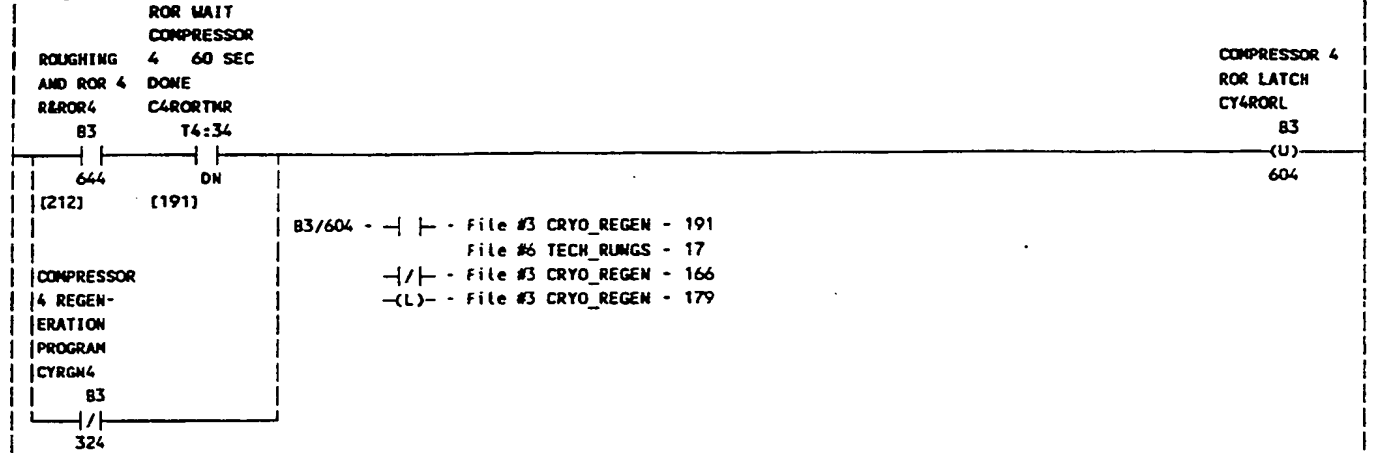


Rung #179

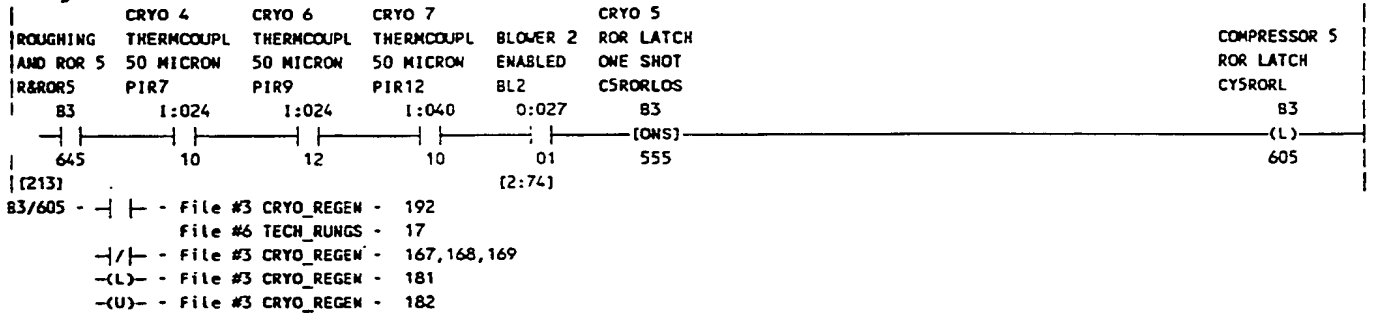


533

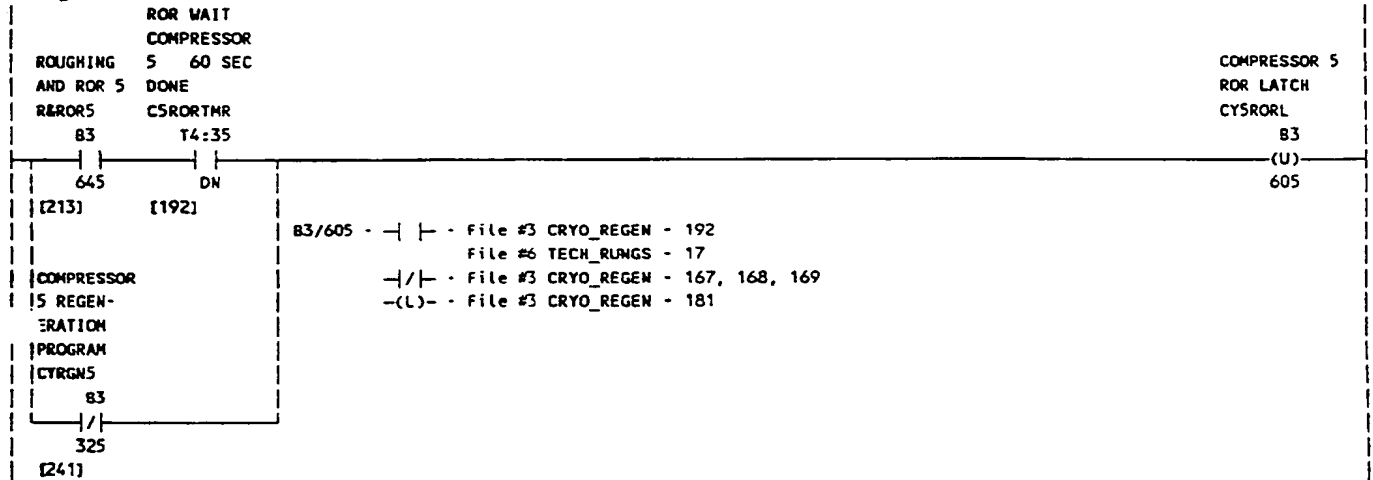
Rung #180



Rung #181

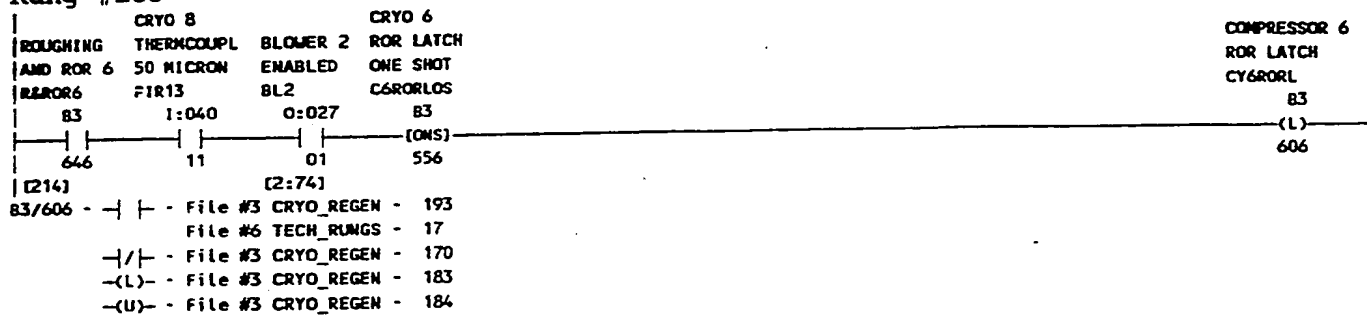


Rung #182

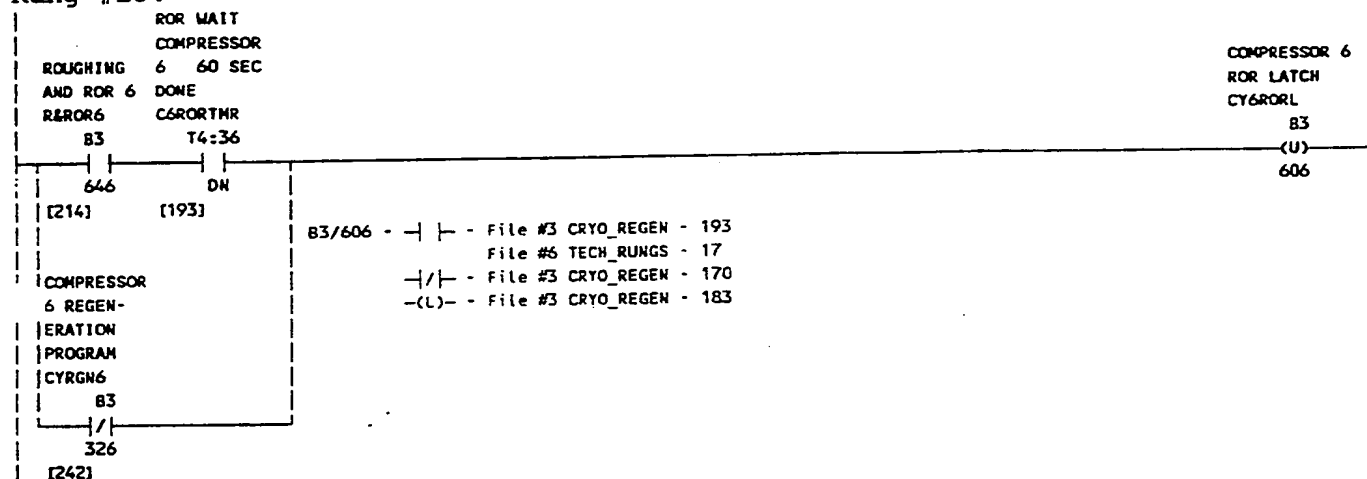


534

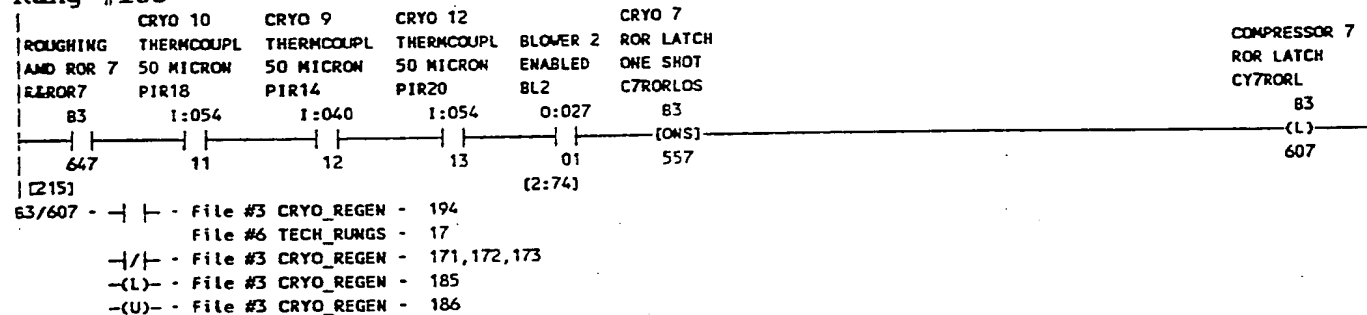
Rung #183



Rung #184

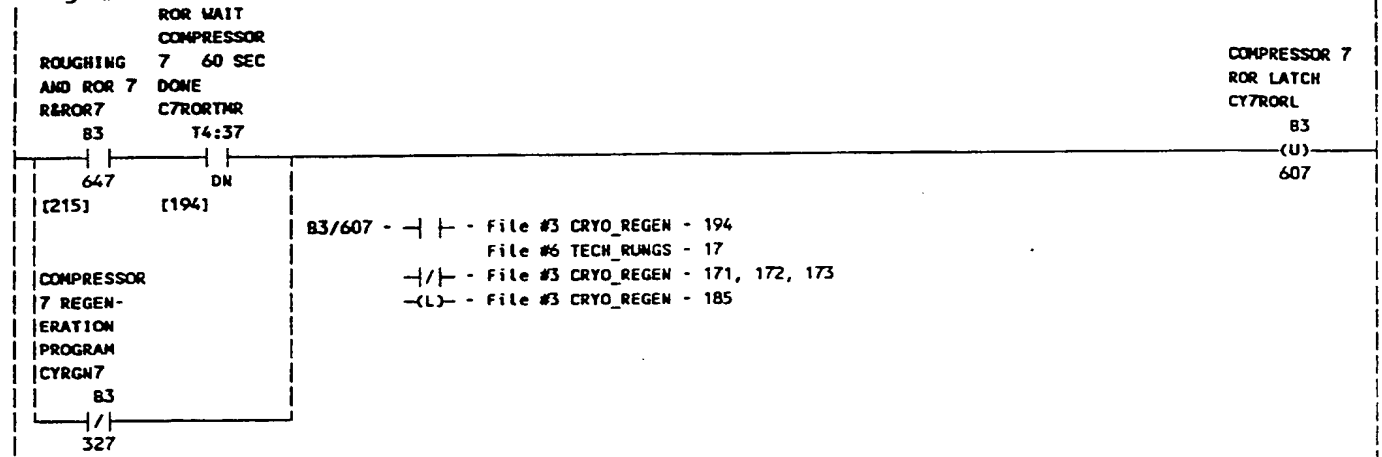


Rung #185

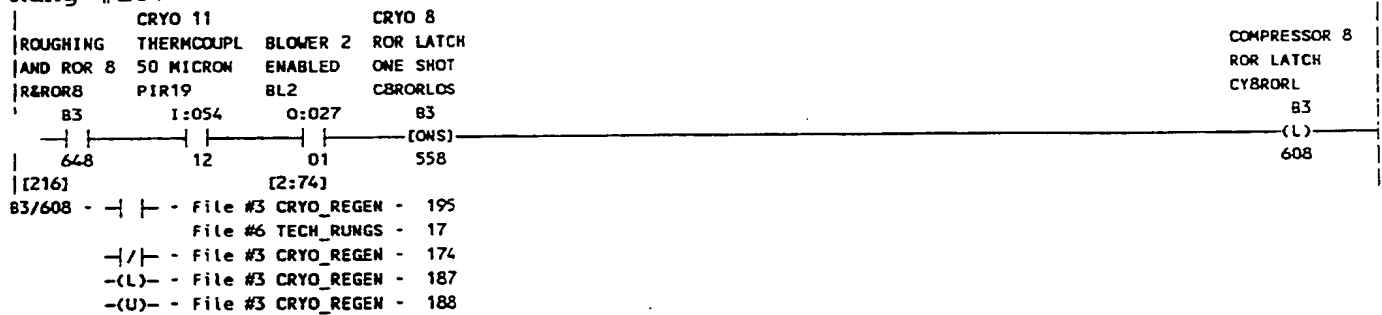


535

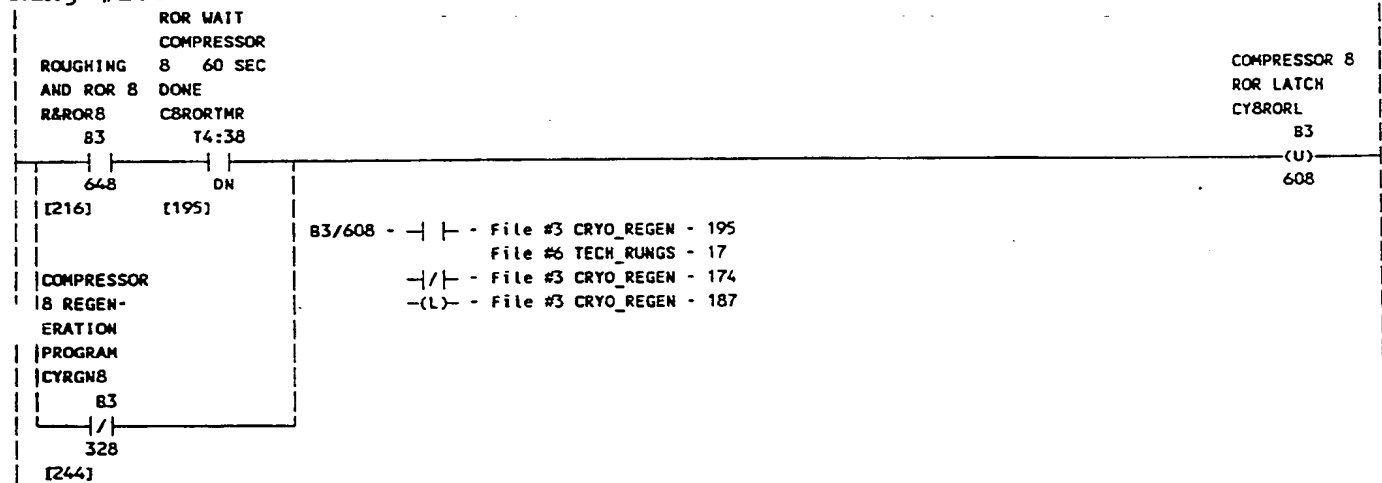
Rung #186



Rung #187



Rung #188



536

Rung #189

ROUGHING COMPRESSOR 2
 AND ROR 2 ROR LATCH
 R&ROR2 CY2RORL

83 83
 642 602
 [210] [176]

ROR WAIT
 COMPRESSOR
 2 60 SEC
 C2RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:32
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:32.DN - | | - File #3 CRYO_REGEN - 176,196,203
 T4:32.TT - | | - File #6 TECH_RUNGS - 18

Rung #190

ROUGHING COMPRESSOR 3
 AND ROR 3 ROR LATCH
 R&ROR3 CY3RORL

83 83
 643 603
 [211] [178]

ROR WAIT
 COMPRESSOR
 3 60 SEC
 C3RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:33
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:33.DN - | | - File #3 CRYO_REGEN - 178,197,204
 3.TT - | | - File #6 TECH_RUNGS - 18

Rung #191

ROUGHING COMPRESSOR 4
 AND ROR 4 ROR LATCH
 R&ROR4 CY4RORL

83 83
 644 604
 [212] [180]

ROR WAIT
 COMPRESSOR
 4 60 SEC
 C4RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:34
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:34.DN - | | - File #3 CRYO_REGEN - 180,198,205
 T4:34.TT - | | - File #6 TECH_RUNGS - 18

Rung #192

ROUGHING COMPRESSOR 5
 AND ROR 5 ROR LATCH
 R&ROR5 CY5RORL

83 83
 645 605
 [213] [182]

ROR WAIT
 COMPRESSOR
 5 60 SEC
 C5RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:35
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:35.DN - | | - File #3 CRYO_REGEN - 182,199,206
 T4:35.TT - | | - File #6 TECH_RUNGS - 18

537

Rung #193

ROUGHING COMPRESSOR 6
 AND ROR 6 ROR LATCH
 R&ROR6 CY6RORL
 83 83
 646 606
 [214] [184]

ROR WAIT
 COMPRESSOR
 6 60 SEC
 C6RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:36
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:36.DN - | | - File #3 CRYO_REGEN - 184,200,207

T4:36.TT - | | - File #6 TECH_RUNGS - 18

Rung #194

ROUGHING COMPRESSOR 7
 AND ROR 7 ROR LATCH
 R&ROR7 CY7RORL
 83 83
 647 607
 [215] [186]

ROR WAIT
 COMPRESSOR
 7 60 SEC
 C7RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:37
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:37.DN - | | - File #3 CRYO_REGEN - 186,201,208

T4:37.TT - | | - File #6 TECH_RUNGS - 18

Rung #195

ROUGHING COMPRESSOR 8
 AND ROR 8 ROR LATCH
 R&ROR8 CY8RORL
 83 83
 648 608
 [216] [188]

ROR WAIT
 COMPRESSOR
 8 60 SEC
 C8RORTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:38
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

T4:38.DN - | | - File #3 CRYO_REGEN - 188,202,209

T4:38.TT - | | - File #6 TECH_RUNGS - 18

Rung #196

ROR WAIT
 COMPRESSOR CRYO 2
 ROUGHING 2 60 SEC THERMCOUPL
 AND ROR 2 DONE 50 MICRON
 R&ROR2 C2RORTMR PIR4
 83 T4:32 1:004
 642 DN 12
 [210] [189]

REROUGH
 COUNTER
 COMPRESSOR
 2
 C2RERUF

CTU
 COUNT UP (CU)
 COUNTER: C5:2
 PRESET: 10 (DN)
 ACCUM: 0

C5:2 - CTU - File #3 CRYO_REGEN - 196

RES - File #3 CRYO_REGEN - 224

C5:2.DN - | | - File #2 MATH_PRGRM - 623,623

538

Rung #197

```

ROR WAIT
COMPRESSOR CRYO 3
ROUGHING 3 60 SEC THERMCOUPL
AND ROR 3 DONE 50 MICRON
R&ROR3 C&RORTMR PIR5
83 T4:33 I:004
|-----|/| |
| 643 | DN | 13 |
| [211] | [190] |

```

```

REROUGH
COUNTER
COMPRESSOR
3
C&SRERUF

```

```

CTU
COUNT UP
COUNTER: CS:3 (CU)
PRESET: 15 (DN)
ACCUM: 0

```

CS:3 - CTU - File #3 CRYO_REGEN - 197

RES - File #3 CRYO_REGEN - 225

CS:3.DN - | | - File #2 MAIN_PRGRM - 623

Rung #198

```

ROR WAIT
COMPRESSOR CRYO 5
ROUGHING 4 60 SEC THERMCOUPL
AND ROR 4 DONE 50 MICRON
R&ROR4 C&RORTMR PIR8
83 T4:34 I:024
|-----|/| |
| 644 | DN | 11 |
| [212] | [191] |

```

```

REROUGH
COUNTER
COMPRESSOR
4
C&RERUF

```

```

CTU
COUNT UP
COUNTER: CS:4 (CU)
PRESET: 10 (DN)
ACCUM: 0

```

4 - CTU - File #3 CRYO_REGEN - 198

RES - File #3 CRYO_REGEN - 226

CS:4.DN - | | - File #2 MAIN_PRGRM - 623

Rung #199

```

ROR WAIT
COMPRESSOR CRYO 4
ROUGHING 5 60 SEC THERMCOUPL
AND ROR 5 DONE 50 MICRON
R&ROR5 C&RORTMR PIR7
83 T4:35 I:024
|-----|/| |
| 645 | DN | 10 |
| [213] | [192] |

```

```

REROUGH
COUNTER
COMPRESSOR
5
C&SRERUF

```

```

CTU
COUNT UP
COUNTER: CS:5 (CU)
PRESET: 10 (DN)
ACCUM: 0

```

CS:5 - RES - File #3 CRYO_REGEN - 227

CS:5.DN - | | - File #2 MAIN_PRGRM - 623

```

CRYO 6
THERMCOUPL
50 MICRON
PIR9
I:024
|-----|/|
| 12 |
CRYO 7
THERMCOUPL
50 MICRON
PIR12
I:040
|-----|/|
| 10 |

```

539

Rung #200

ROR WAIT
COMPRESSOR CRYO 8
ROUGHING 6 60 SEC THERMCOUPL
AND ROR 6 DONE 50 MICRON
R&ROR6 C&RORTMR PIR13
B3 T4:36 I:040

646 DN 11
[214] [193]

REROUGH
COUNTER
COMPRESSOR
6
C&R3RUF

CTU
COUNT UP (CU)
COUNTER: CS:6
PRESET: 10 (DN)
ACCUM: 0

CS:6 - CTU - File #3 CRYO_REGEN - 200

RES - File #3 CRYO_REGEN - 228

CS:6.DN - | | - File #2 MATH_PRGRM - 623

Rung #201

ROR WAIT
COMPRESSOR CRYO 9
ROUGHING 7 60 SEC THERMCOUPL
AND ROR 7 DONE 50 MICRON
R&ROR7 C7RORTMR PIR14
B3 T4:37 I:040

647 DN 12
[215] [194]

REROUGH
COUNTER
COMPRESSOR
7
C7RERUF

CTU
COUNT UP (CU)
COUNTER: CS:7
PRESET: 10 (DN)
ACCUM: 0

CS:7 - RES - File #3 CRYO_REGEN - 229

CS:7.DN - | | - File #2 MATH_PRGRM - 623

CRYO 10
THERMCOUPL
50 MICRON
PIR18
I:054

11.

CRYO 12
THERMCOUPL
50 MICRON
PIR20
I:054

13

Rung #202

ROR WAIT
COMPRESSOR CRYO 11
ROUGHING 8 60 SEC THERMCOUPL
AND ROR 8 DONE 50 MICRON
R&ROR8 C&RORTMR PIR19
B3 T4:38 I:054

648 DN 12
[161] [195]

REROUGH
COUNTER
COMPRESSOR
8
C&R8RUF

CTU
COUNT UP (CU)
COUNTER: CS:8
PRESET: 10 (DN)
ACCUM: 0

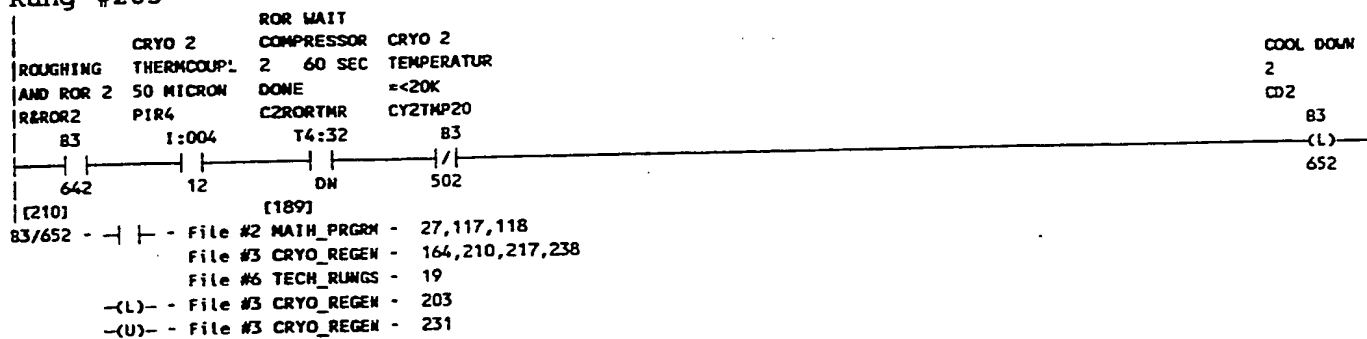
CS:8 - CTU - File #3 CRYO_REGEN - 202

RES - File #3 CRYO_REGEN - 230

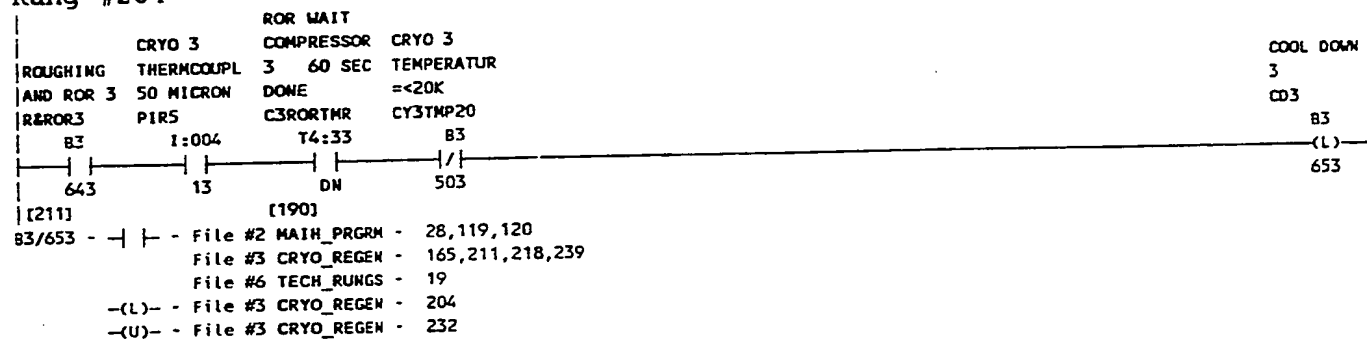
CS:8.DN - | | - File #2 MATH_PRGRM - 623

540

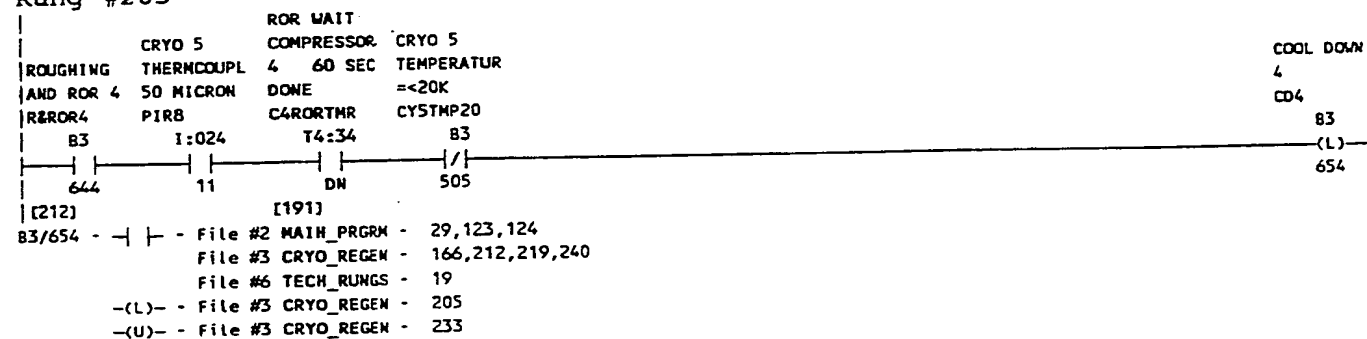
Rung #203



Rung #204

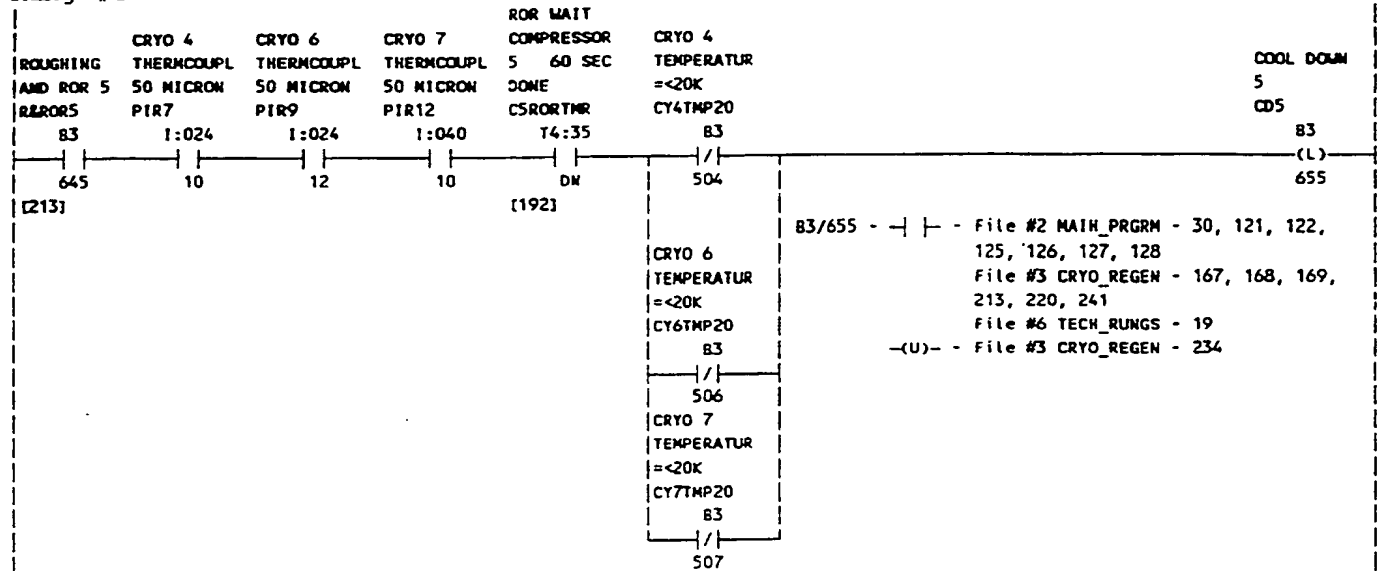


Rung #205

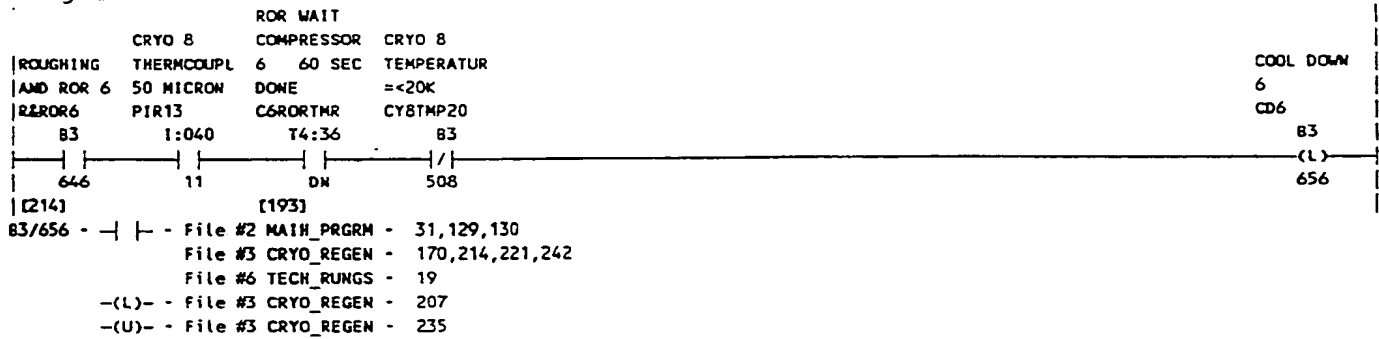


541

Rung #206

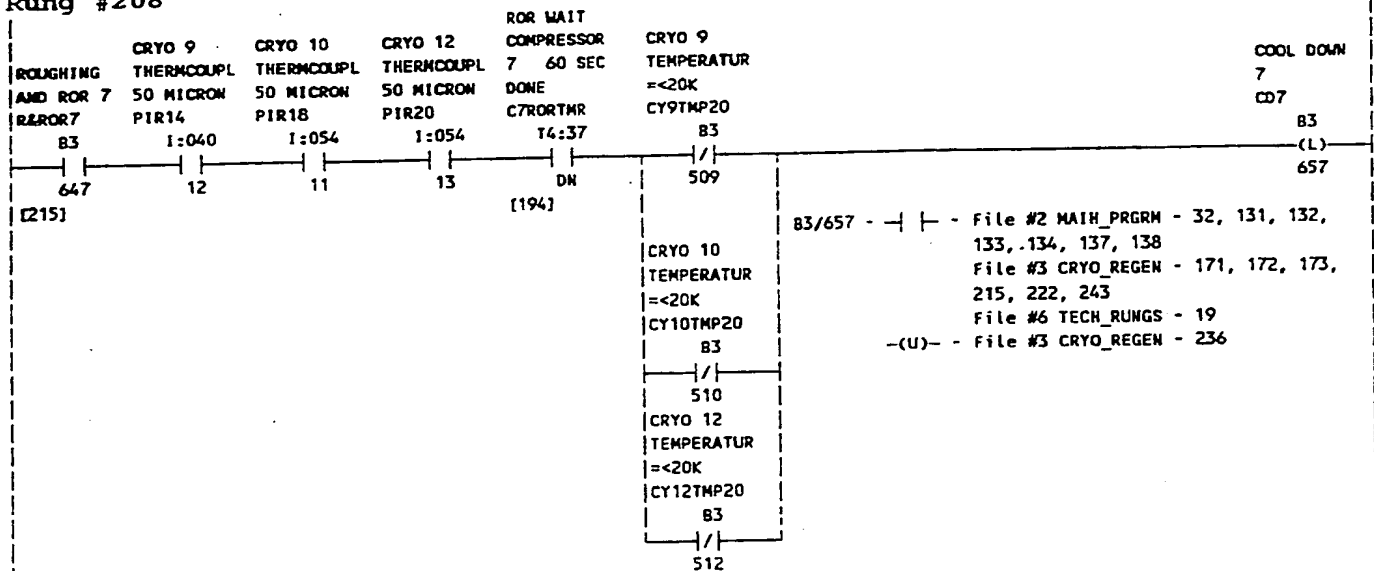


Rung #207

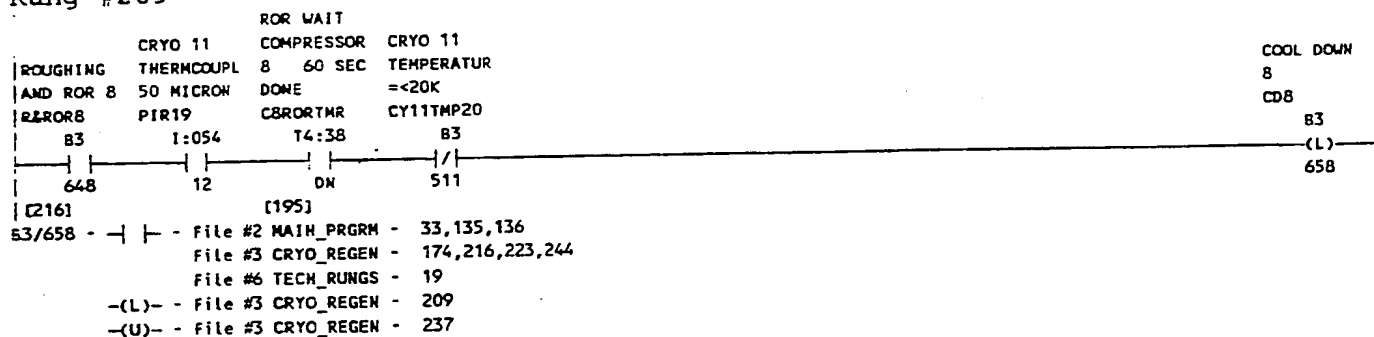


542

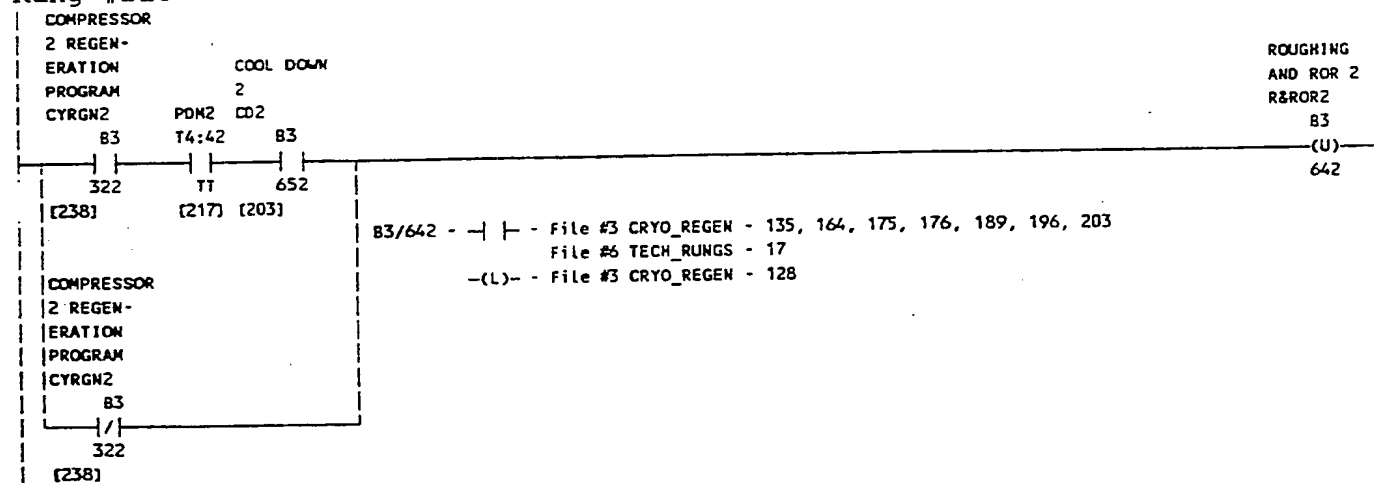
Rung #208



Rung #209



Rung #210



543

Rung #211

COMPRESSOR

3 REGEN-

ERATION

PROGRAM

CYRGN3

COOL DOWN

3

PDM3 CD3

B3

T4:43

B3

[239]

323

TT

[218]

653

[204]

B3/643 - | | - File #3 CRYO_REGEN - 136, 165, 177, 178, 190, 197, 204
 File #6 TECH_RUNGS - 17
 -(L)- - File #3 CRYO_REGEN - 129

COMPRESSOR

3 REGEN-

ERATION

PROGRAM

CYRGN3

B3

/

323

[239]

ROUGHING

AND ROR 3

R&ROR3

B3

(U)

643

Rung #212

COMPRESSOR

4 REGEN-

ERATION

PROGRAM

CYRGN4

COOL DOWN

4

PDM4 CD4

B3

T4:44

B3

[240]

324

TT

[219]

654

[205]

B3/644 - | | - File #3 CRYO_REGEN - 137, 166, 179, 180, 191, 198, 205
 File #6 TECH_RUNGS - 17
 -(L)- - File #3 CRYO_REGEN - 130

COMPRESSOR

4 REGEN-

ERATION

PROGRAM

CYRGN4

B3

/

324

[240]

ROUGHING

AND ROR 4

R&ROR4

B3

(U)

644

Rung #213

COMPRESSOR

5 REGEN-

ERATION

PROGRAM

CYRGN5

COOL DOWN

5

PDM5 CD5

B3

T4:45

B3

[241]

325

TT

[220]

655

[206]

B3/645 - | | - File #3 CRYO_REGEN - 138, 167, 168, 169, 181, 182, 192, 199, 206
 File #6 TECH_RUNGS - 17
 -(L)- - File #3 CRYO_REGEN - 131

COMPRESSOR

5 REGEN-

ERATION

PROGRAM

CYRGN5

B3

/

325

[241]

ROUGHING

AND ROR 5

R&ROR5

B3

(U)

645

545

Rung #217

CRYO 2
 COOL DOWN TEMPERATUR
 2
 = <20K
 CD2 CY2TMP20
 B3 B3
 652 502
 [203]

REGEN
 TIME TO
 20K 2
 PDM2
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:42
 BASE (SEC): 1.0 (DN)
 PRESET: 7200
 ACCUM: 0

T4:42.DN - | | - File #3 CRYO_REGEN - 32,252
 T4:42.TT - | | - File #3 CRYO_REGEN - 210

Rung #218

CRYO 3
 COOL DOWN TEMPERATUR
 3
 = <20K
 CD3 CY3TMP20
 B3 B3
 653 503
 [204]

REGEN
 TIME TO
 20K 3
 PDM3
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:43
 BASE (SEC): 1.0 (DN)
 PRESET: 7200
 ACCUM: 0

T4:43.DN - | | - File #3 CRYO_REGEN - 32,253
 T4:43.TT - | | - File #3 CRYO_REGEN - 211

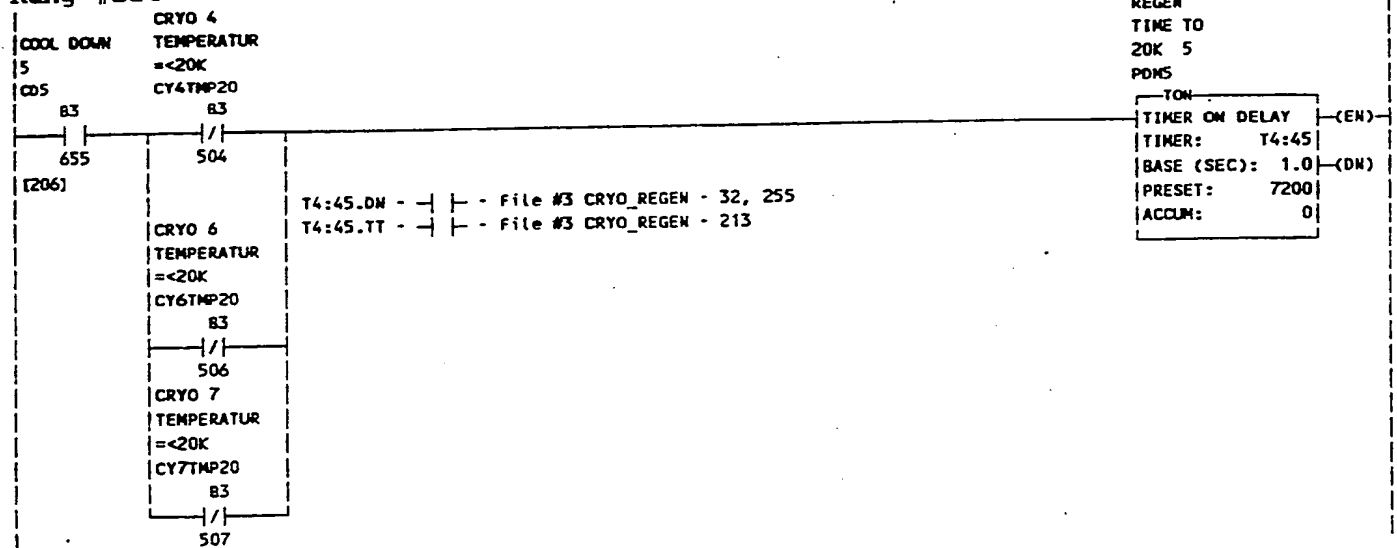
Rung #219

CRYO 5
 COOL DOWN TEMPERATUR
 4
 = <20K
 CD4 CY5TMP20
 B3 B3
 654 505
 [205]

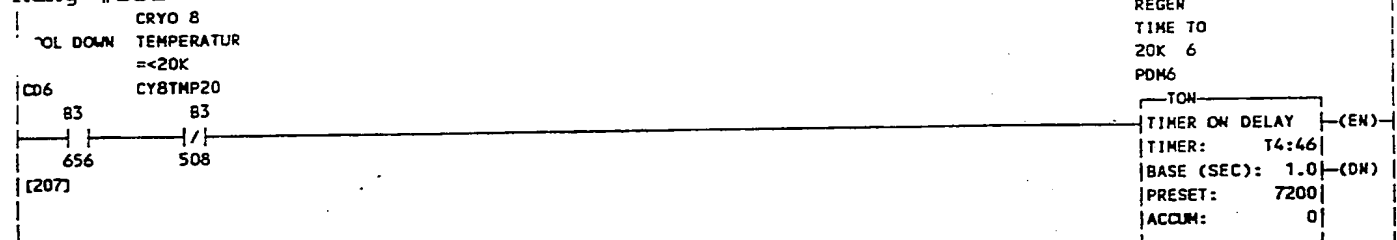
REGEN
 TIME TO
 20K 4
 PDM4
 TON
 TIMER ON DELAY (EN)
 TIMER: T4:44
 BASE (SEC): 1.0 (DN)
 PRESET: 7200
 ACCUM: 0

T4:44.DN - | | - File #3 CRYO_REGEN - 32,254
 T4:44.TT - | | - File #3 CRYO_REGEN - 212

Rung #220

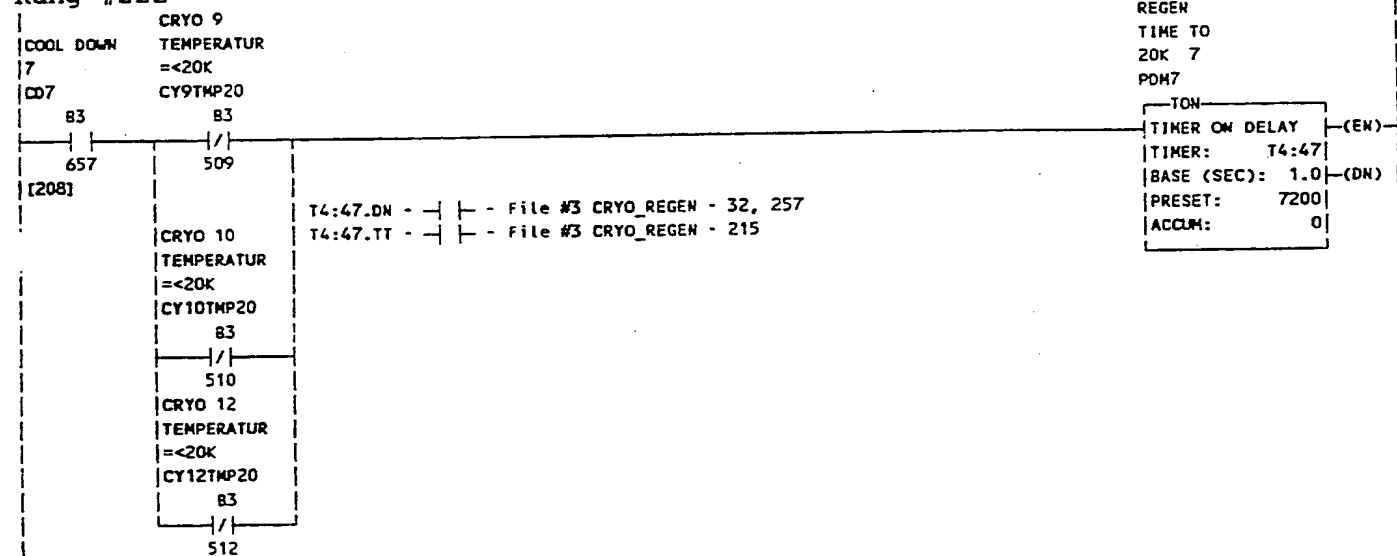


Rung #221



T4:46.DN - - File #3 CRYO_REGEN - 32,256
T4:46.TT - - File #3 CRYO_REGEN - 214

Rung #222



547

Rung #223

CRYO 11
COOL DOWN TEMPERATUR
8 = <20K
CD8 CY11TMP20
83 83
658 511
[209]

REGEN
TIME TO
20K 8
PDMS

TON
TIMER ON DELAY (EN)
TIMER: T4:48
BASE (SEC): 1.0 (DN)
PRESET: 7200
ACCLM: 0

T4:48.DN - | | - File #3 CRYO_REGEN - 32,258
T4:48.TT - | | - File #3 CRYO_REGEN - 216

BASE : Rung #224

COMPRESSOR CRYO 2
2 REGEN- COUNTER
ERATION RESET
PROGRAM ONE SHOT
CYRGN2 C2CROS
83 83
322 562
[238]

REROUGH
COUNTER
COMPRESSOR
2
C2RERUF
C5:2
(RES)

C5:2 - CTU - File #3 CRYO_REGEN - 196
C5:2.DN - | | - File #2 MAIN_PRGRM - 624

PAUSE
DISABLE
TS12
N7:16
4
[2:3]

548

BASE : Rung #225

COMPRESSOR CRYO 3
3 REGEN- COUNTER
ERATION RESET
PROGRAM ONE SHOT
CYRGN3 C3CROS

83 83

|/| [ONS]

323 563

[239]

PAUSE
DISABLE
TS12
N7:16

4

[2:3]

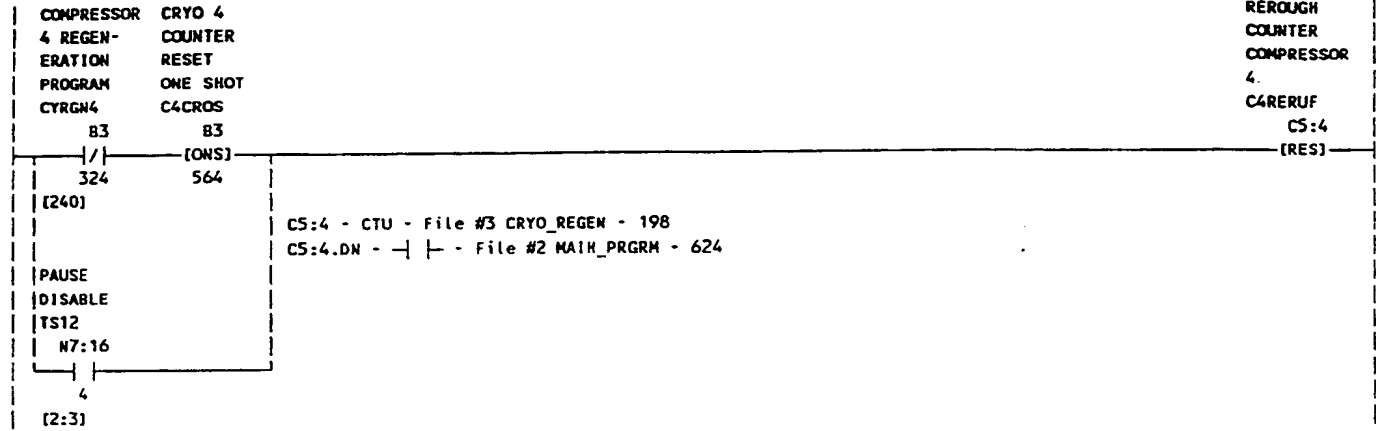
C5:3 - CTU - File #3 CRYO_REGEN - 197
C5:3.DN - | - File #2 MAIN_PRGRM - 624

REROUGH
COUNTER
COMPRESSOR
3
C3RERUF

C5:3

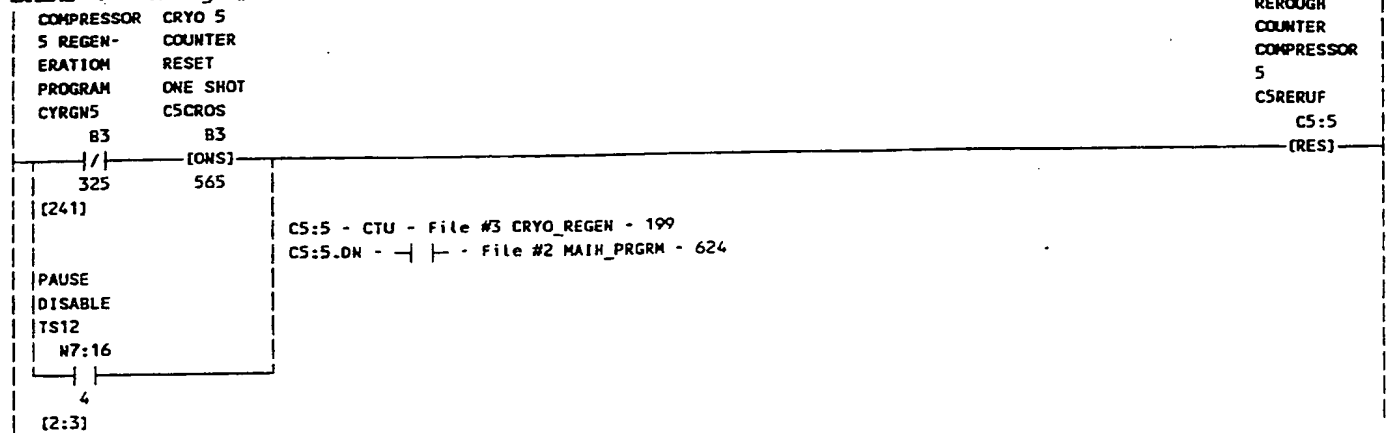
[RES]

BASE : Rung #226



550

BASE : Rung #227



551

BASE : Rung #228

COMPRESSOR CRYO 6
6 REGEN- COUNTER
ERATION RESET
PROGRAM ONE SHOT
CYRGN6 C6CROS

REROUGH
COUNTER
COMPRESSOR
6
C6R3RUF

83 83

CS:6

326 566

[RES]

[242]

CS:6 - CTU - File #3 CRYO_REGEN - 200
CS:6.DN - - File #2 MAIN_PRGRM - 624

PAUSE

DISABLE

TS12

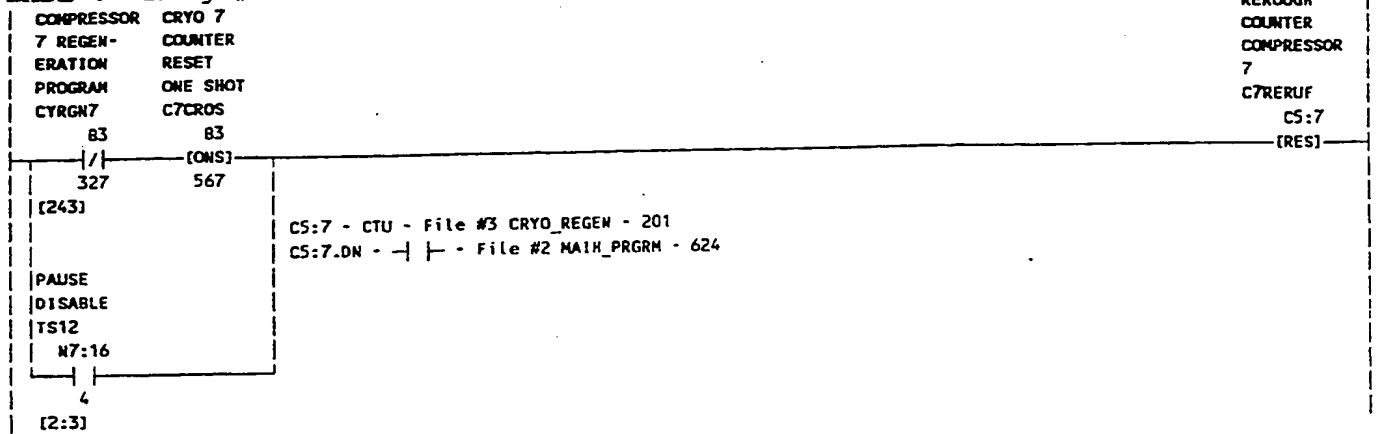
M7:16

4

[2:3]

552

BASE : Rung #229



BASE : Rung #230

COMPRESSOR CRYO 8
 8 REGEN- COUNTER
 ERATION RESET
 PROGRAM ONE SHOT
 CYRGN8 C8CROS

REROUGH
 COUNTER
 COMPRESSOR
 8
 C8RERUF

83 83

CS:8

328 568

[RES]

[244]

CS:8 - CTU - File #3 CRYO_REGEN - 202
 CS:8.DN - - File #2 MAIN_PRGRM - 624

PAUSE

DISABLE

TS12

N7:16

4

[2:3]

Rung #231

COMPRESSOR

2 REGEN-

ERATION

PROGRAM

CYRGN2

83

322

COOL DOWN

2

CD2

83

(U)

652

[238]

83/652 - - File #2 MAIN_PRGRM - 27,117,118
 File #3 CRYO_REGEN - 164,210,217,238
 File #6 TECH_RUNGS - 19
 -(L)- - File #3 CRYO_REGEN - 203
 -(U)- - File #3 CRYO_REGEN - 231

554

Rung #232

COMPRESSOR
3 REGEN-
ERATION
PROGRAM
CYRGN3

COOL DOWN
3
CD3

B3
|/|
323

B3
(U)
653

[239]

83/653 - | | - File #2 MATH_PRGRM - 28,119,120
File #3 CRYO_REGEN - 165,211,218,239
File #6 TECH_RUNGS - 19
-(L)- - File #3 CRYO_REGEN - 204
-(U)- - File #3 CRYO_REGEN - 232

Rung #233

COMPRESSOR
4 REGEN-
ERATION
PROGRAM
CYRGN4

COOL DOWN
4
CD4

B3
|/|
324

B3
(U)
654

[240]

83/654 - | | - File #2 MATH_PRGRM - 29,123,124
File #3 CRYO_REGEN - 166,212,219,240
File #6 TECH_RUNGS - 19
-(L)- - File #3 CRYO_REGEN - 205
-(U)- - File #3 CRYO_REGEN - 233

Rung #234

COMPRESSOR
5 REGEN-
ERATION
PROGRAM
CYRGN5

COOL DOWN
5
CD5

B3
|/|
325

B3
(U)
655

[241]

83/655 - | | - File #2 MATH_PRGRM - 30,121,122,125,126,127,128
File #3 CRYO_REGEN - 167,168,169,213,220,241
File #6 TECH_RUNGS - 19
-(L)- - File #3 CRYO_REGEN - 206
-(U)- - File #3 CRYO_REGEN - 234

Rung #235

COMPRESSOR
6 REGEN-
ERATION
PROGRAM
CYRGN6

COOL DOWN
6
CD6

B3
|/|
326

B3
(U)
656

[242]

83/656 - | | - File #2 MATH_PRGRM - 31,129,130
File #3 CRYO_REGEN - 170,214,221,242
File #6 TECH_RUNGS - 19
-(L)- - File #3 CRYO_REGEN - 207
-(U)- - File #3 CRYO_REGEN - 235

555

Rung #236

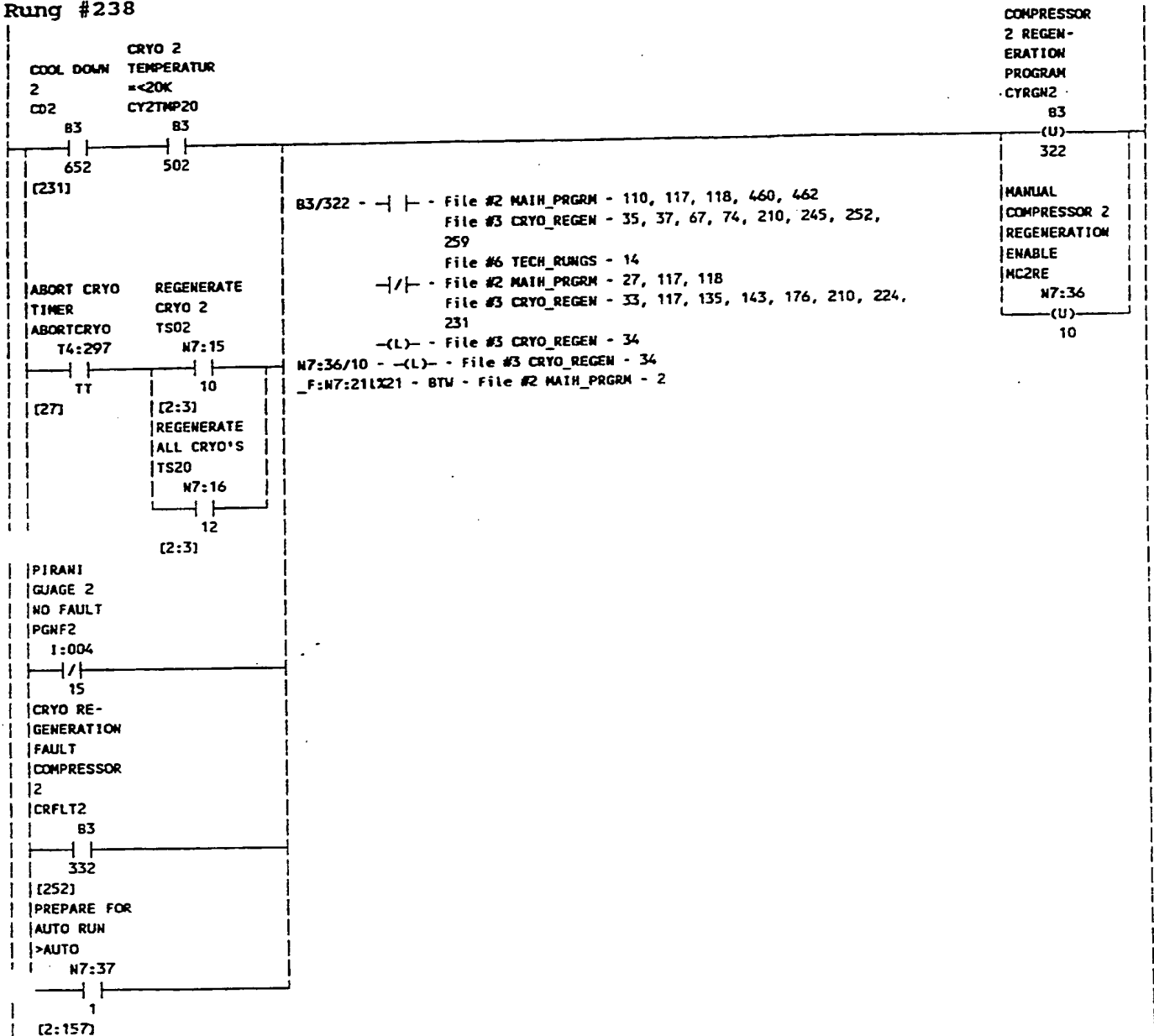
COMPRESSOR		
7 REGEN-		
ERATION		COOL DOWN
PROGRAM		7
CYRGN7		CD7
83		83
/		(U)
327		657
[243]		
83/657 - -	File #2 MAIN_PRGRM - 32,131,132,133,134,137,138	
	File #3 CRYO_REGEN - 171,172,173,215,222,243	
	File #6 TECH_RUNGS - 19	
	-(L)- File #3 CRYO_REGEN - 208	
	-(U)- File #3 CRYO_REGEN - 236	

Rung #237

COMPRESSOR		
8 REGEN-		
ERATION		COOL DOWN
PROGRAM		8
CYRGN8		CD8
83		83
/		(U)
328		658
[244]		
83/658 - -	File #2 MAIN_PRGRM - 33,135,136	
	File #3 CRYO_REGEN - 174,216,223,244	
	File #6 TECH_RUNGS - 19	
	-(L)- File #3 CRYO_REGEN - 209	
	-(U)- File #3 CRYO_REGEN - 237	

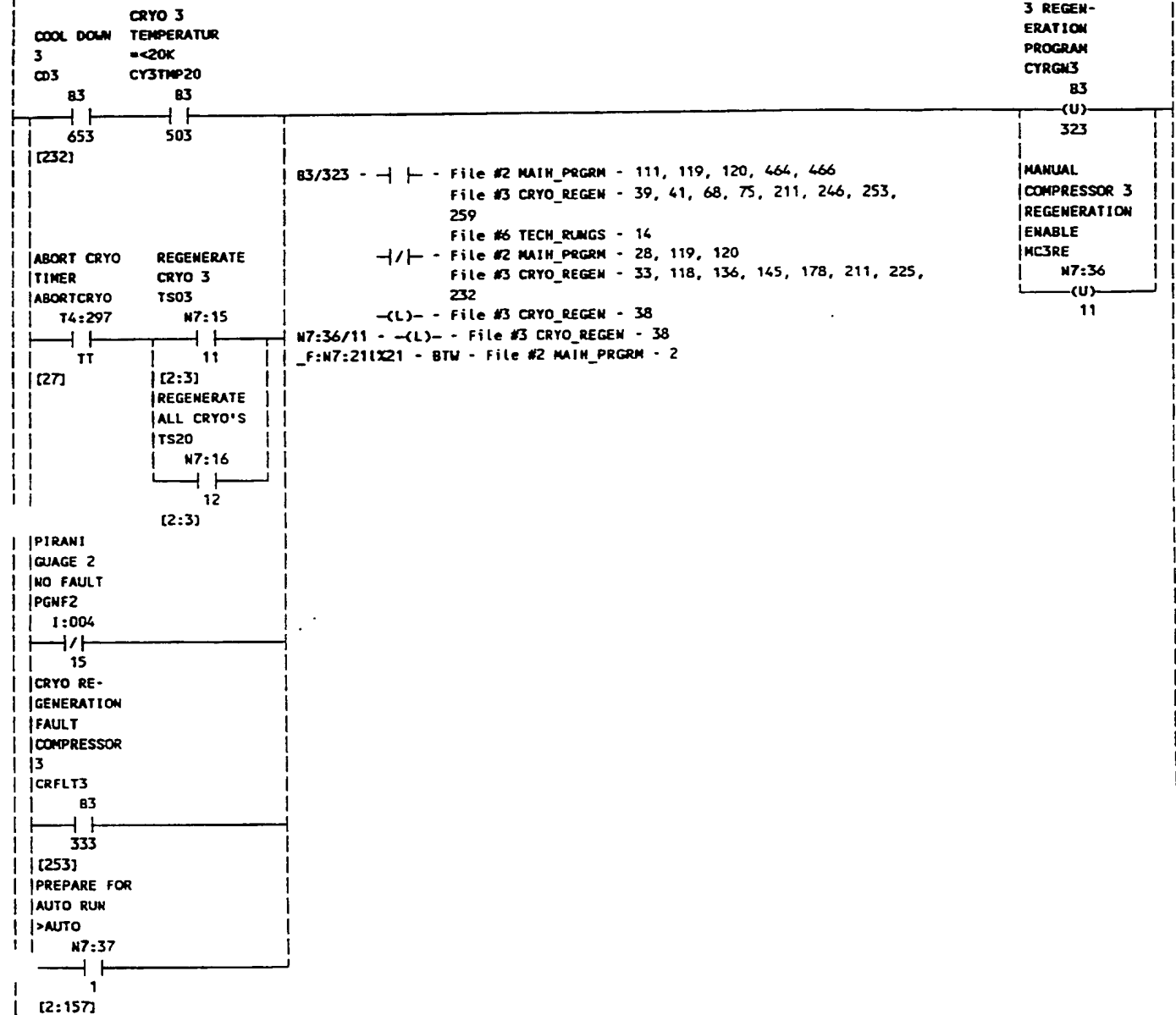
556

Rung #238



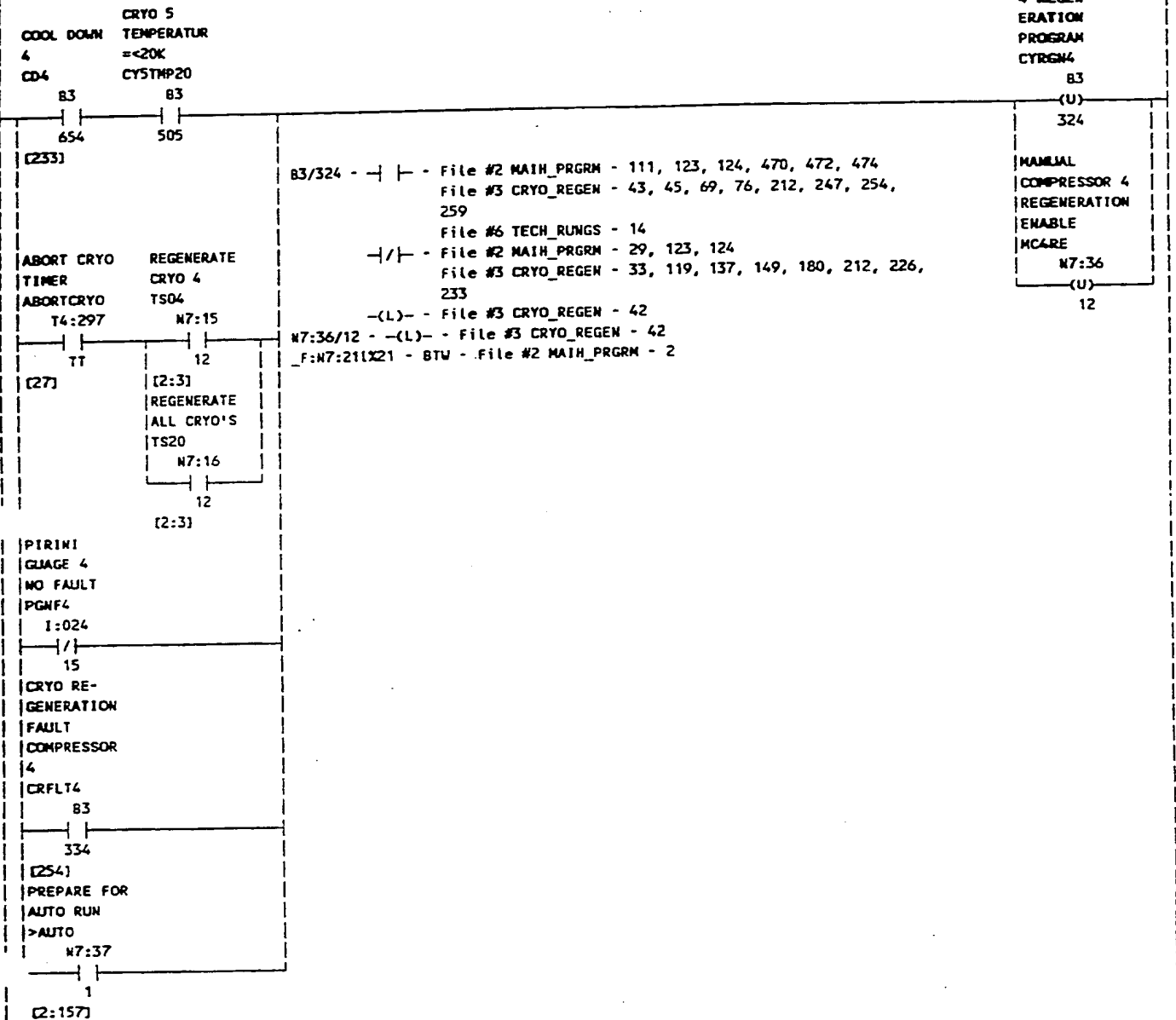
557

Rung #239



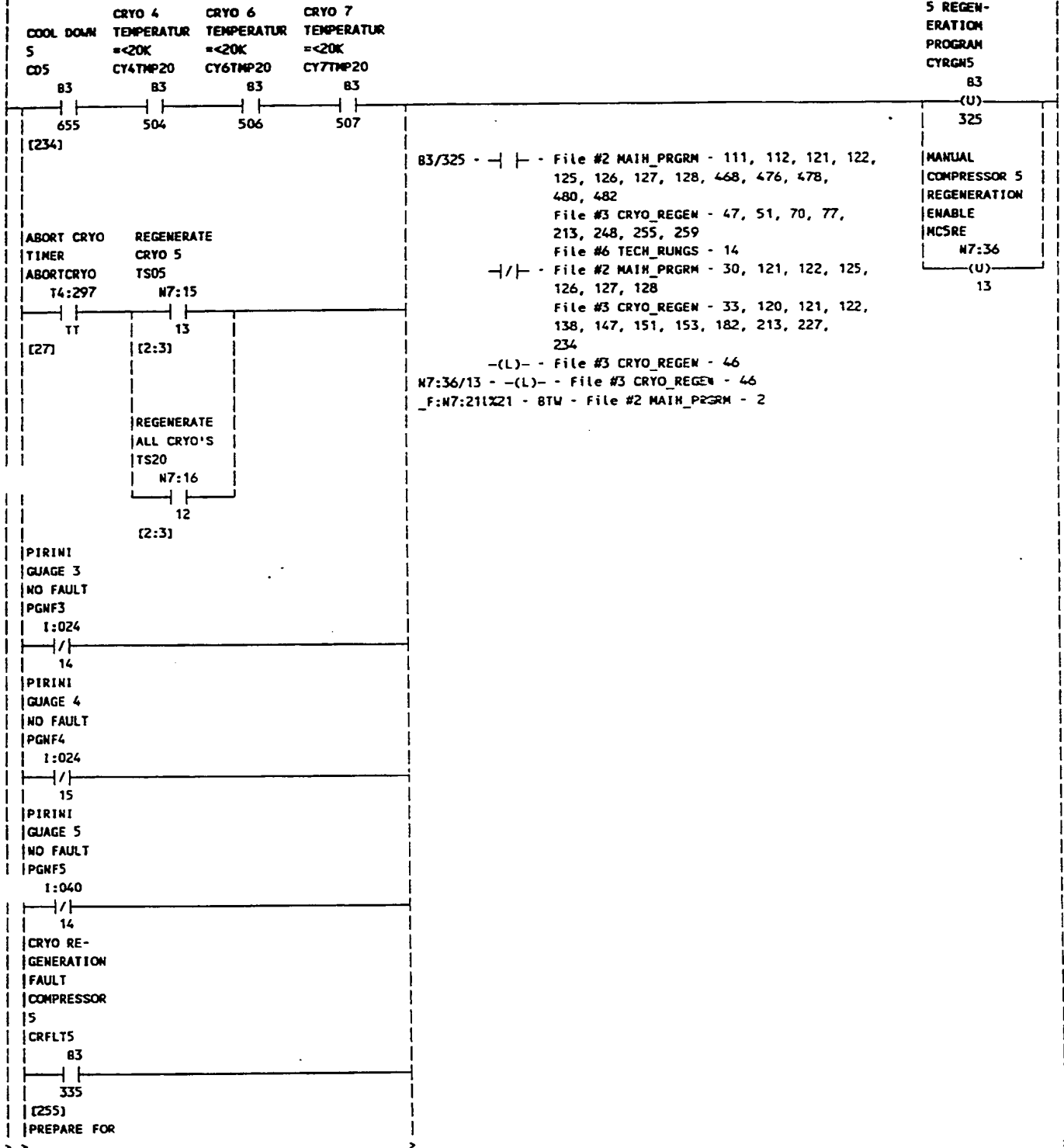
558

Rung #240

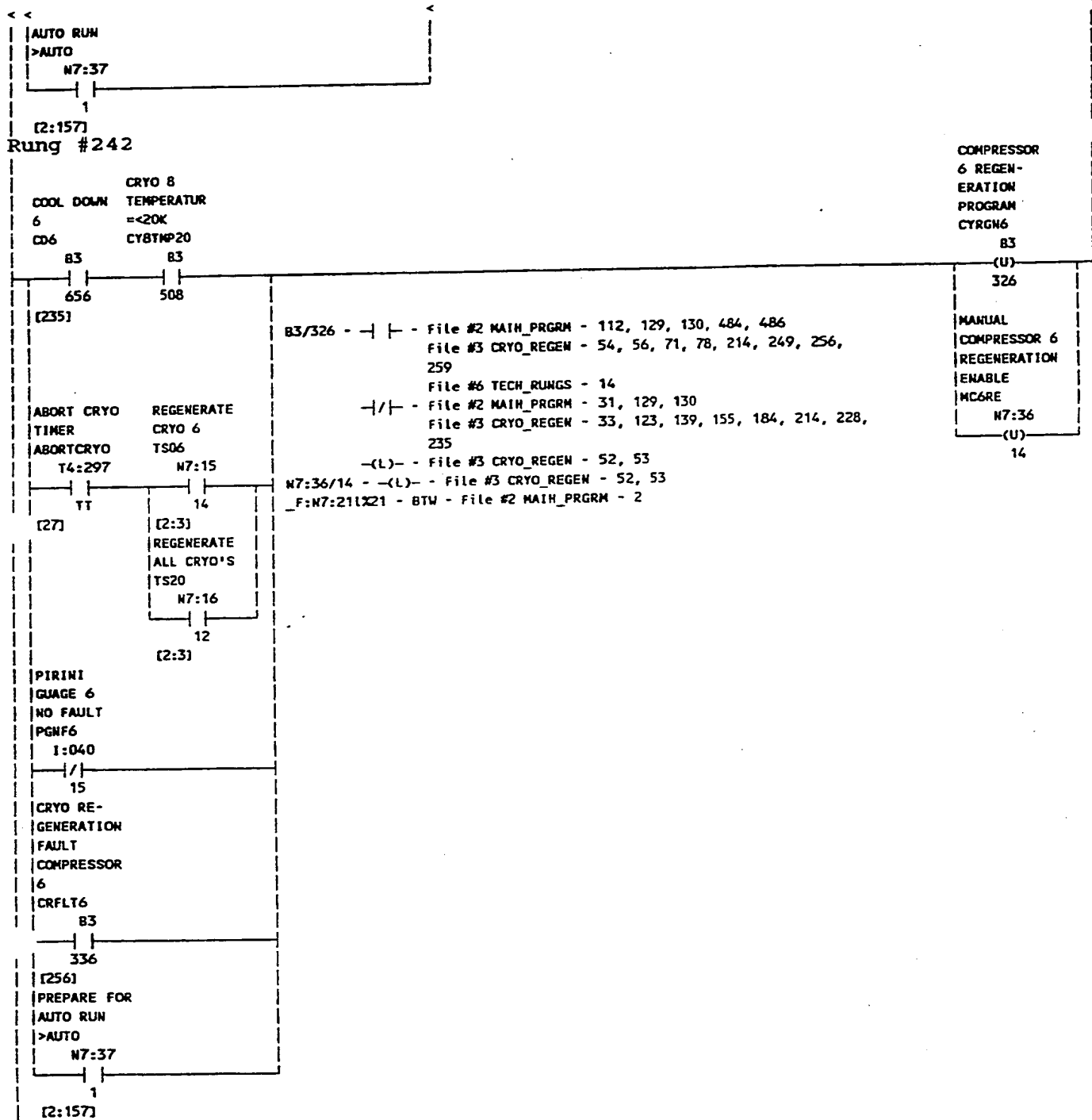


559

Rung #241

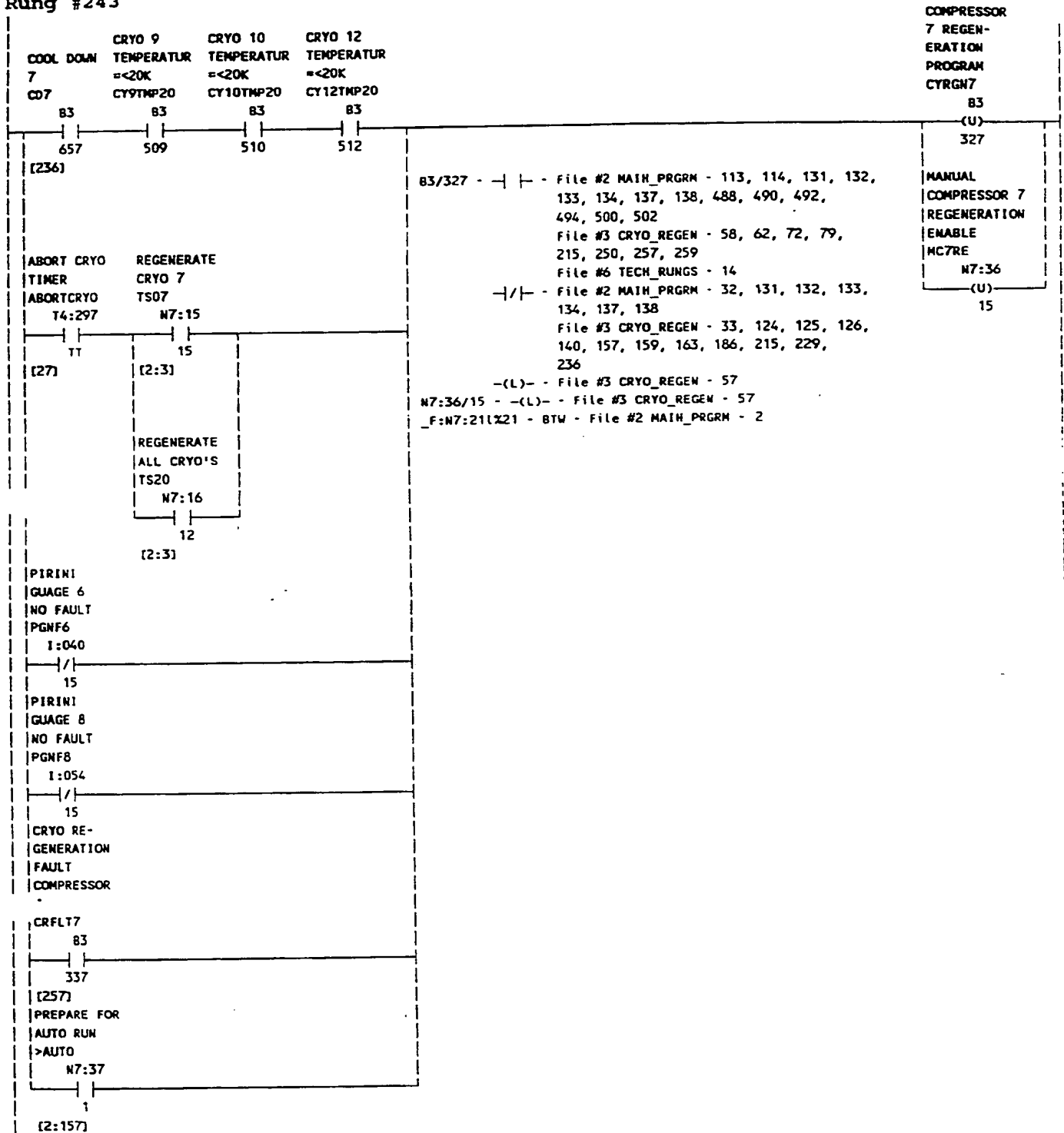


560



561

Rung #243



562

Rung #244

CRYO 11
COOL DOWN TEMPERATUR
8 = <20K
CD8 CY11TMP20

B3 83
658 511

[237]

ABORT CRYO REGENERATE
TIMER CRYO 8
ABORTCRYO TS08
T4:297 N7:16

TT 0

[27]

[2:3]
REGENERATE
ALL CRYO'S
TS20

N7:16

12

[2:3]

PIRINI
GUAGE 8
NO FAULT
PGNF8
1:054

15

CRYO RE-
GENERATION
FAULT
COMPRESSOR
8

CRFLT8
83

338

[258]

PREPARE FOR
AUTO RUN
>AUTO

N7:37

1

[2:157]

B3/328 - | | - File #2 MAIN_PRGRM - 113, 135, 136, 496, 498
File #3 CRYO_REGEN - 64, 66, 73, 80, 216, 251, 258, 259
File #6 TECH_RUNGS - 14
-|/| - File #2 MAIN_PRGRM - 33, 135, 136
File #3 CRYO_REGEN - 33, 127, 141, 161, 188, 216, 230, 237
-(L)- File #3 CRYO_REGEN - 63
N7:37/0 - -(L)- File #3 CRYO_REGEN - 63
_F:N7:211X21 - BTW - File #2 MAIN_PRGRM - 2

COMPRESSOR
8 REGEN-
ERATION
PROGRAM
CYRGW8

83

(U)

328

MANUAL
COMPRESSOR 8
REGENERATION
ENABLE
MC8RE

N7:37

(U)

0

Rung #245

COMPRESSOR HEATER 2
2 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSE
CYRGN2 HV2S1

83 1:004
322 00
[238]

CRYO REGEN
COMPRESSOR
2 HV2 FAULT
CR2FLT

TIMER ON DELAY (EN)
TIMER: T4:12
BASE (SEC): 1.0 (DN)
PRESET: 30
ACCUM: 0

T4:12.DN - | - File #3 CRYO_REGEN - 252

Rung #246

COMPRESSOR DWELL 1
3 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSED
CYRGN3 HV3S1

83 1:004
323 03
[239]

CRYO REGEN
COMPRESSOR
3 HV3 FAULT
CR3FLT

TIMER ON DELAY (EN)
TIMER: T4:13
BASE (SEC): 1.0 (DN)
PRESET: 30
ACCUM: 0

13.DN - | - File #3 CRYO_REGEN - 253

Rung #247

COMPRESSOR HEATER 3
4 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSED
CYRGN4 HV5S1

83 1:024
324 00
[240]

CRYO REGEN
COMPRESSOR
4 HV5 FAULT
CR5FLT

TIMER ON DELAY (EN)
TIMER: T4:14
BASE (SEC): 1.0 (DN)
PRESET: 30
ACCUM: 0

T4:14.DN - | - File #3 CRYO_REGEN - 254

564

Rung #248

COMPRESSOR DWELL 2
 5 REGEN- CHAMBER
 ERATION GATE VALVE
 PROGRAM CLOSED
 CYRGN5 HV4S1

83 1:022
 325 06
 [241]

DWELL 3
 CHAMBER
 GATE VALVE
 CLOSED
 HV6S1

1:024

03

DWELL 4
 CHAMBER
 GATE VALVE
 CLOSED
 HV7S1

1:036

06

T4:15.DN - | - File #3 CRYO_REGEN - 255

CRYO REGEN
 COMPRESSOR
 5 HV4,6,7 FAULT
 CR467FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:15
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

Rung #249

COMPRESSOR BUFFER 3
 5 REGEN- CHAMBER
 ERATION GATE VALVE
 PROGRAM CLOSED
 CYRGN6 HV8S1

83 1:040
 326 00
 [242]

CRYO REGEN
 COMPRESSOR
 6 HV8 FAULT
 CR8FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:16
 BASE (SEC): 1.0 (DN)
 PRESET: 30
 ACCUM: 0

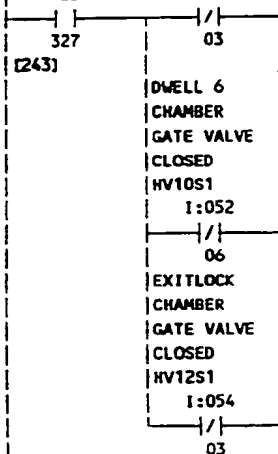
T4:16.DN - | - File #3 CRYO_REGEN - 256

565

Rung #250

COMPRESSOR DWELL 5
7 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSED
CYRGN7 HV9S1

B3 I:040



T4:17.DN - - File #3 CRYO_REGEN - 257

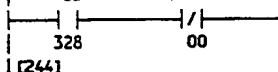
CRYO REGEN
COMPRESSOR
7 HV91012 FAULT
CR91012FLT.

TON
TIMER ON DELAY (EN)
TIMER: T4:17
BASE (SEC): 1.0 (DN)
PRESET: 30
ACCUM: 0

Rung #251

COMPRESSOR BUFFER 4
7 REGEN- CHAMBER
ERATION GATE VALVE
PROGRAM CLOSED
CYRGN8 HV11S1

B3 I:054



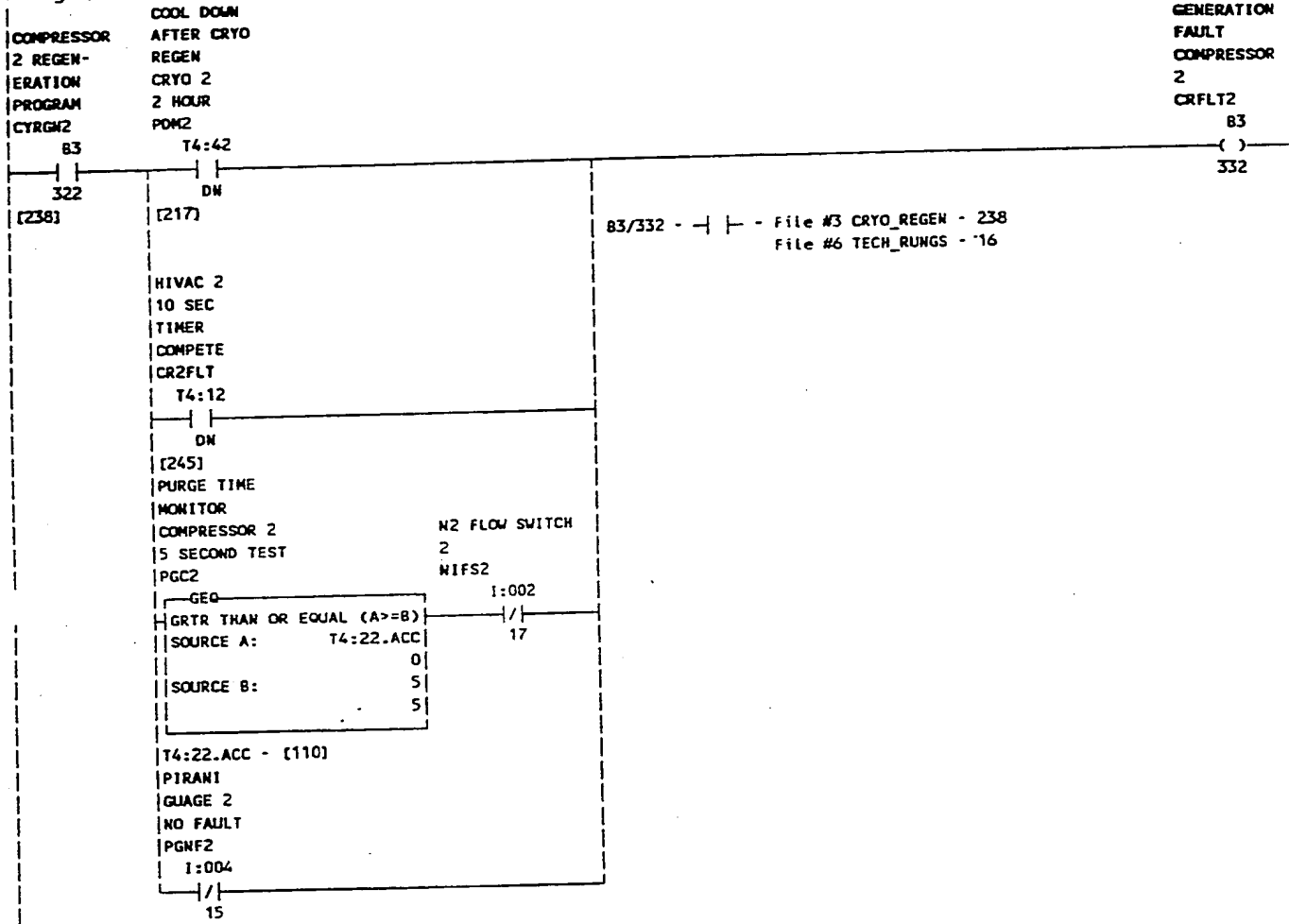
CRYO REGEN
COMPRESSOR
8 HV11 FAULT
CR11FLT

TON
TIMER ON DELAY (EN)
TIMER: T4:18
BASE (SEC): 1.0 (DN)
PRESET: 30
ACCUM: 0

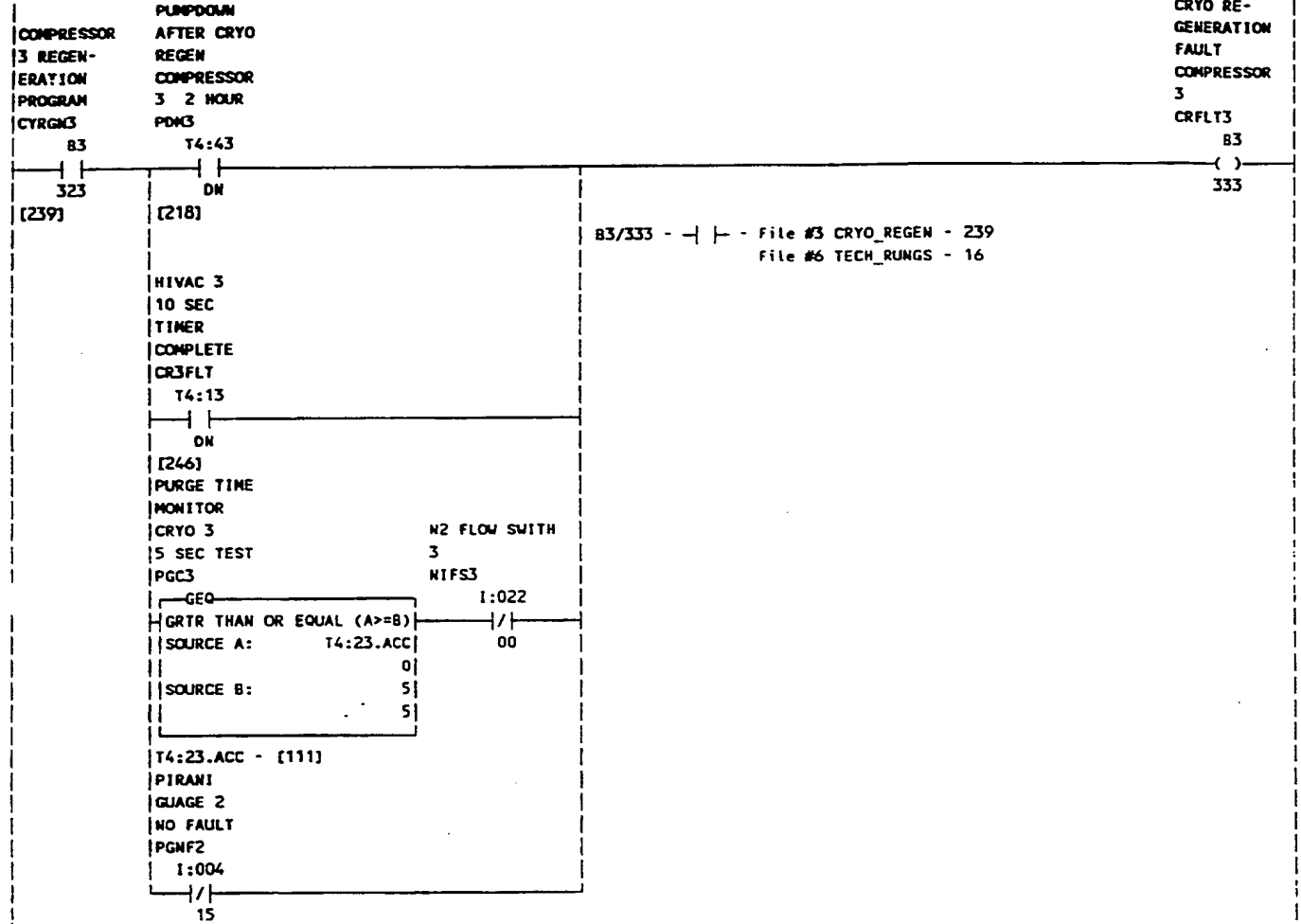
T4:18.DN - - File #3 CRYO_REGEN - 258

566

Rung #252

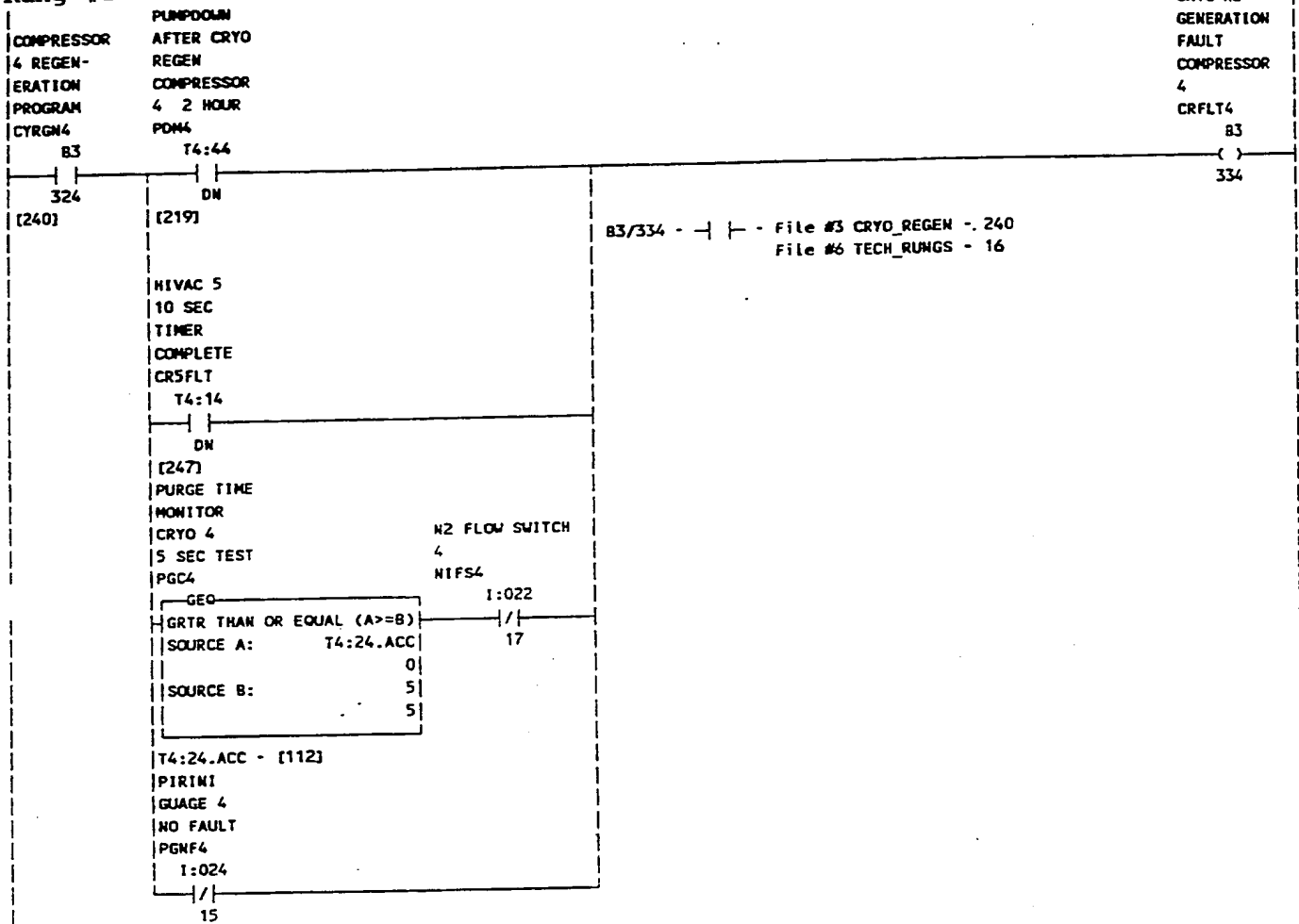


Rung #253



568

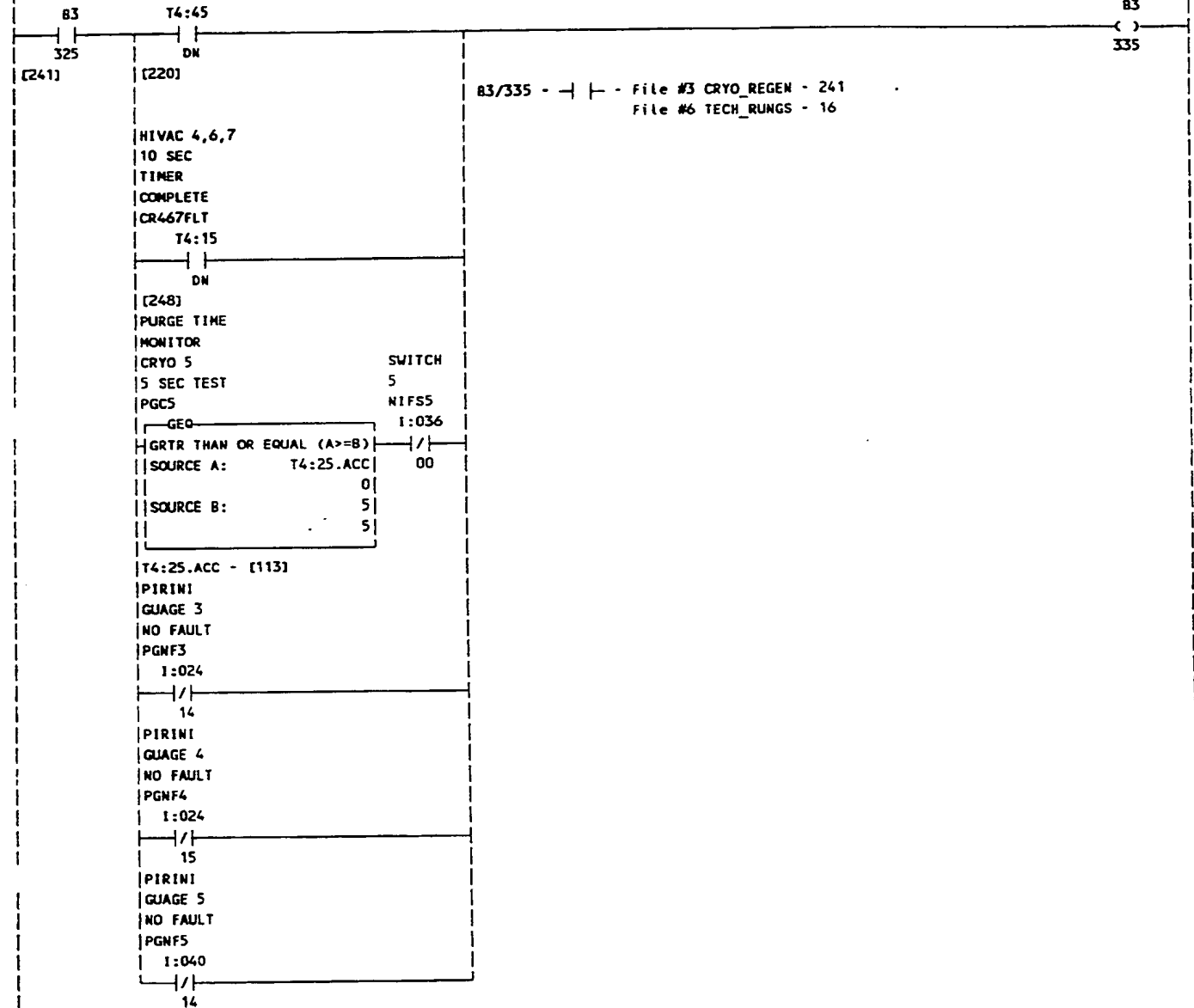
Rung #254



Rung #255

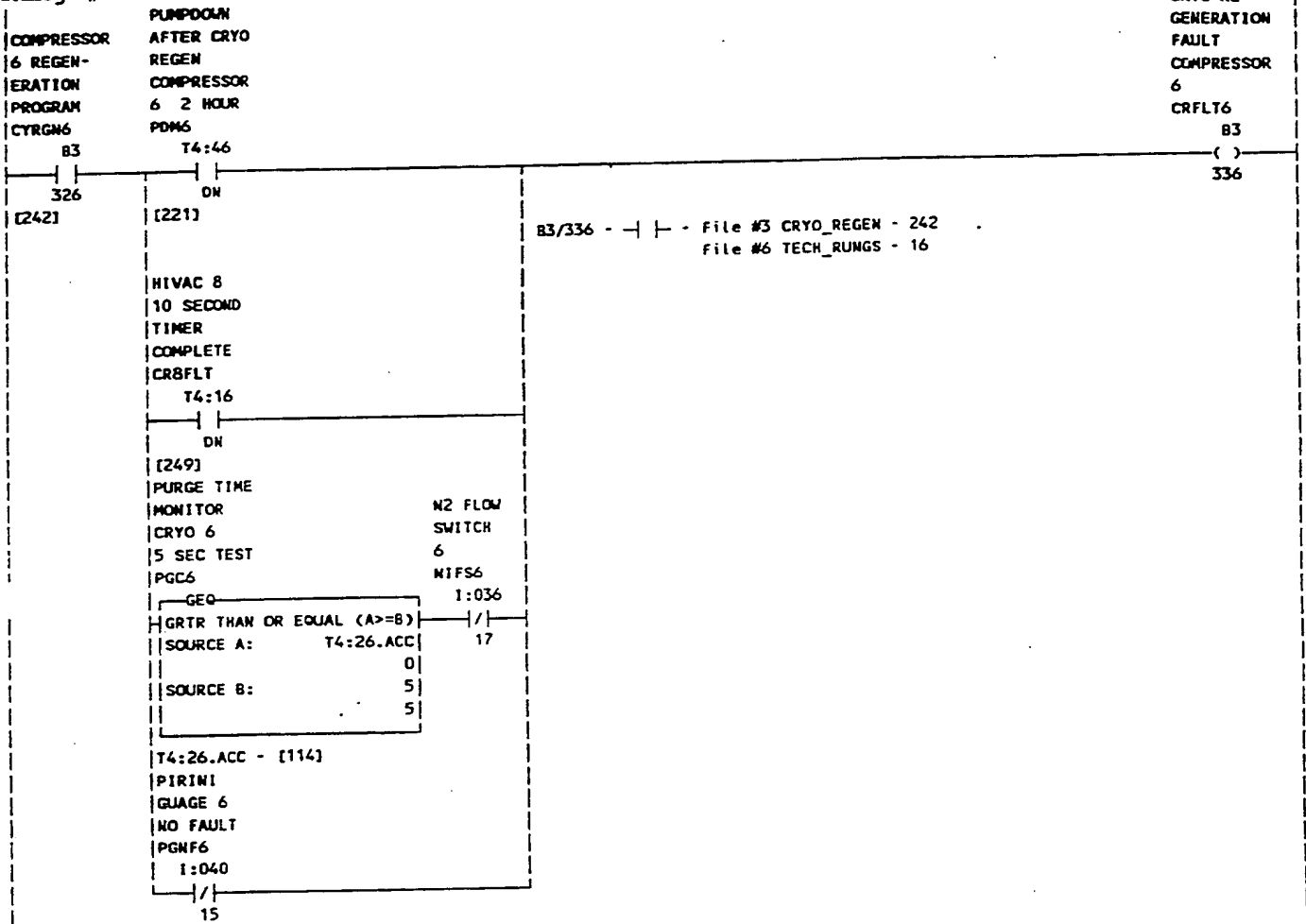
COMPRESSOR AFTER CRYO
5 REGEN- REGEN
ERATION COMPRESSOR
PROGRAM 5 2 HOUR
CYRGH5 PDH5

CRYO RE-
GENERATION
FAULT
COMPRESSOR
5
CRFLT5

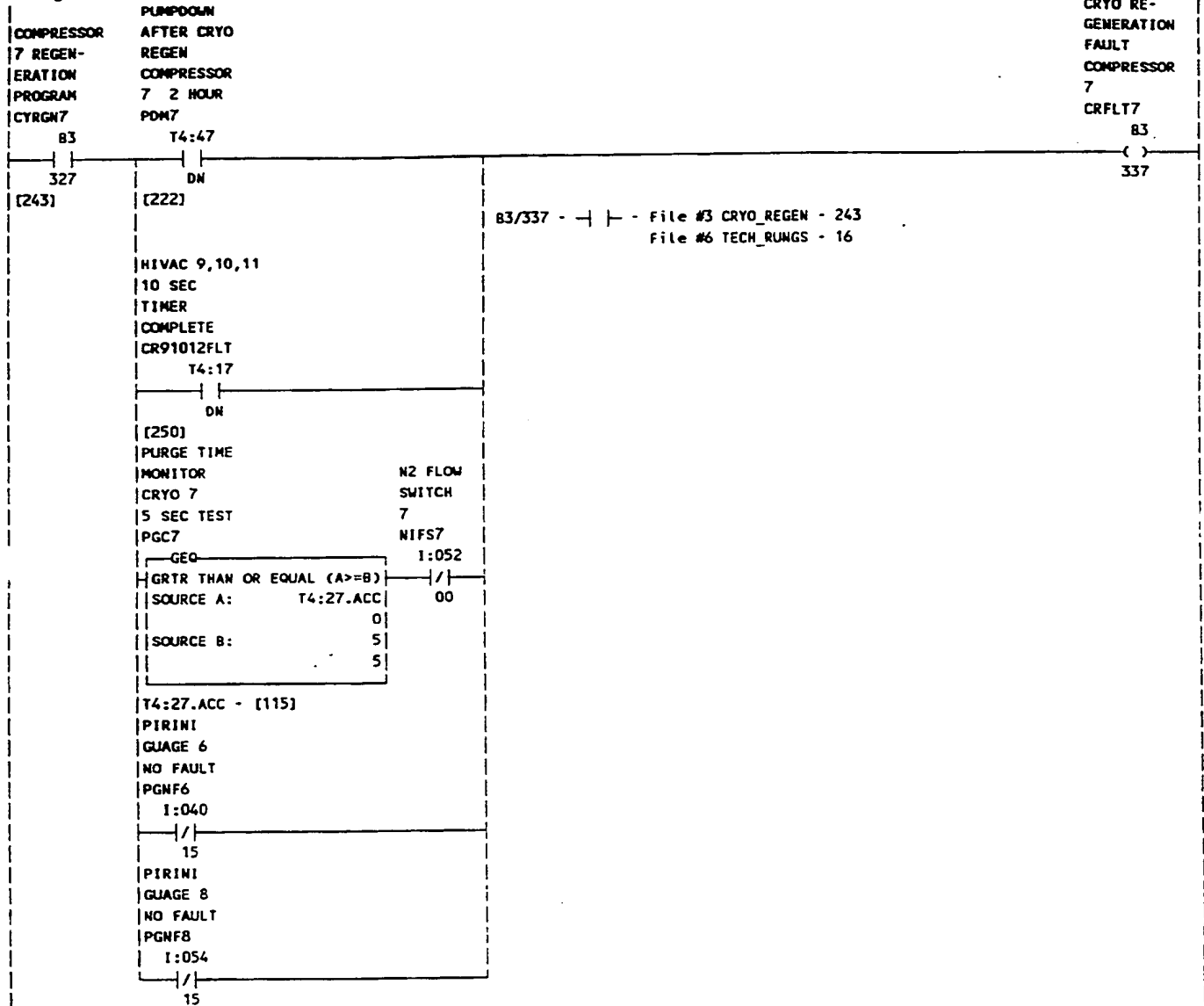


570

Rung #256

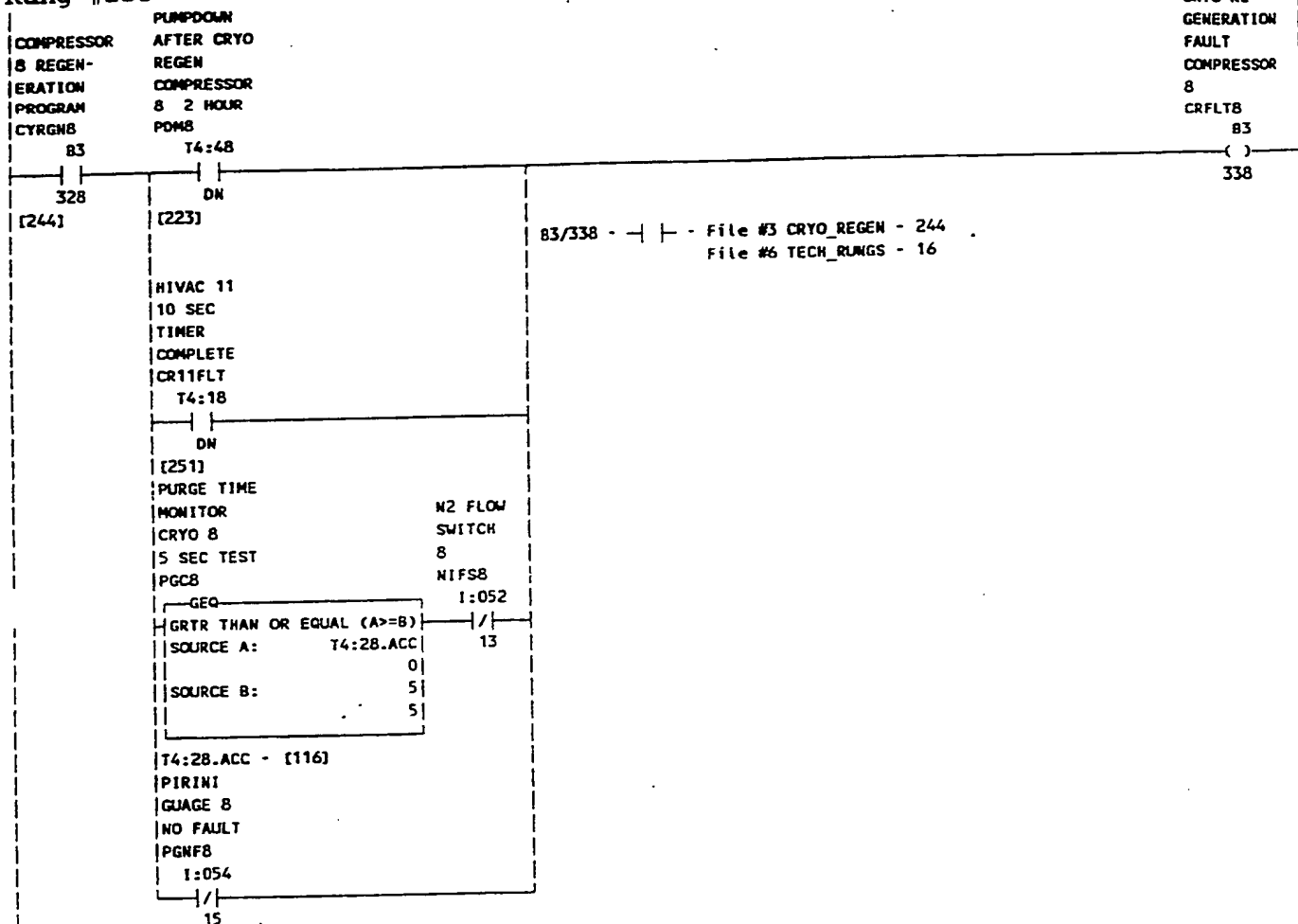


Rung #257



572

Rung #258



Rung #259

COMPRESSOR

1 REGEN-

ERATION

PROGRAM

CYRGN1

83

REGEN-

ERATION

'OR'

RGN_OR

83

321

[25]

83/316 - - File #3 CRYO_REGEN - 260

COMPRESSOR

2 REGEN-

ERATION

PROGRAM

CYRGN2

83

322

[238]

COMPRESSOR

3 REGEN-

ERATION

PROGRAM

CYRGN3

83

323

[239]

COMPRESSOR

4 REGEN-

ERATION

PROGRAM

CYRGN4

83

324

[240]

COMPRESSOR

5 REGEN-

ERATION

PROGRAM

CYRGN5

83

325

[241]

COMPRESSOR

6 REGEN-

ERATION

PROGRAM

CYRGN6

83

326

[242]

COMPRESSOR

7 REGEN-

ERATION

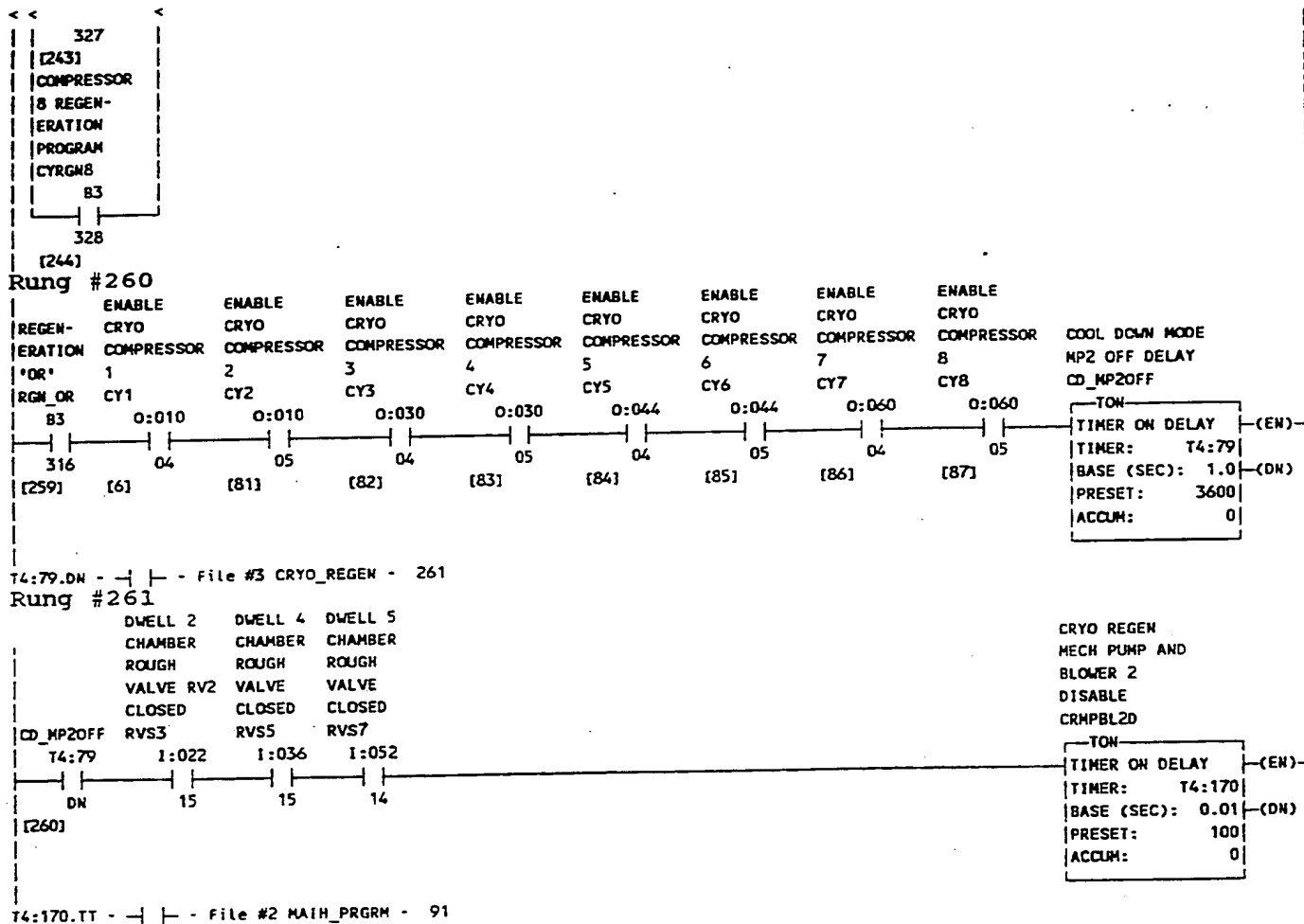
PROGRAM

CYRGN7

83

316

574



575

Rung #262

PURGE TIME
MONITOR
CRYO 1
60 MIN
DONE
PGC1

T4:21

DN

[9]

PURGE TIME
MONITOR
CRYO 2
120 MIN.
DONE
PGC2

T4:22

DN

[110]

PURGE TIME
MONITOR
CRYO 3
120 MIN.
DONE
PGC3

T4:23

DN

[111]

PURGE TIME
MONITOR
CRYO 4
120 MIN
DONE
PGC4

T4:24

DN

[112]

PURGE TIME
MONITOR
CRYO 5
120 MIN
DONE
PGC5

T4:25

DN

[113]

PURGE TIME
MONITOR
CRYO 6
120 MIN
DONE
PGC6

T4:26

DN

[114]

PURGE TIME

PURGE COMPLETE
PRGDONE

TON

TIMER ON DELAY	(EN)
TIMER: T4:130	
BASE (SEC): 1.0	(DN)
PRESET: 10	
ACCU: 0	

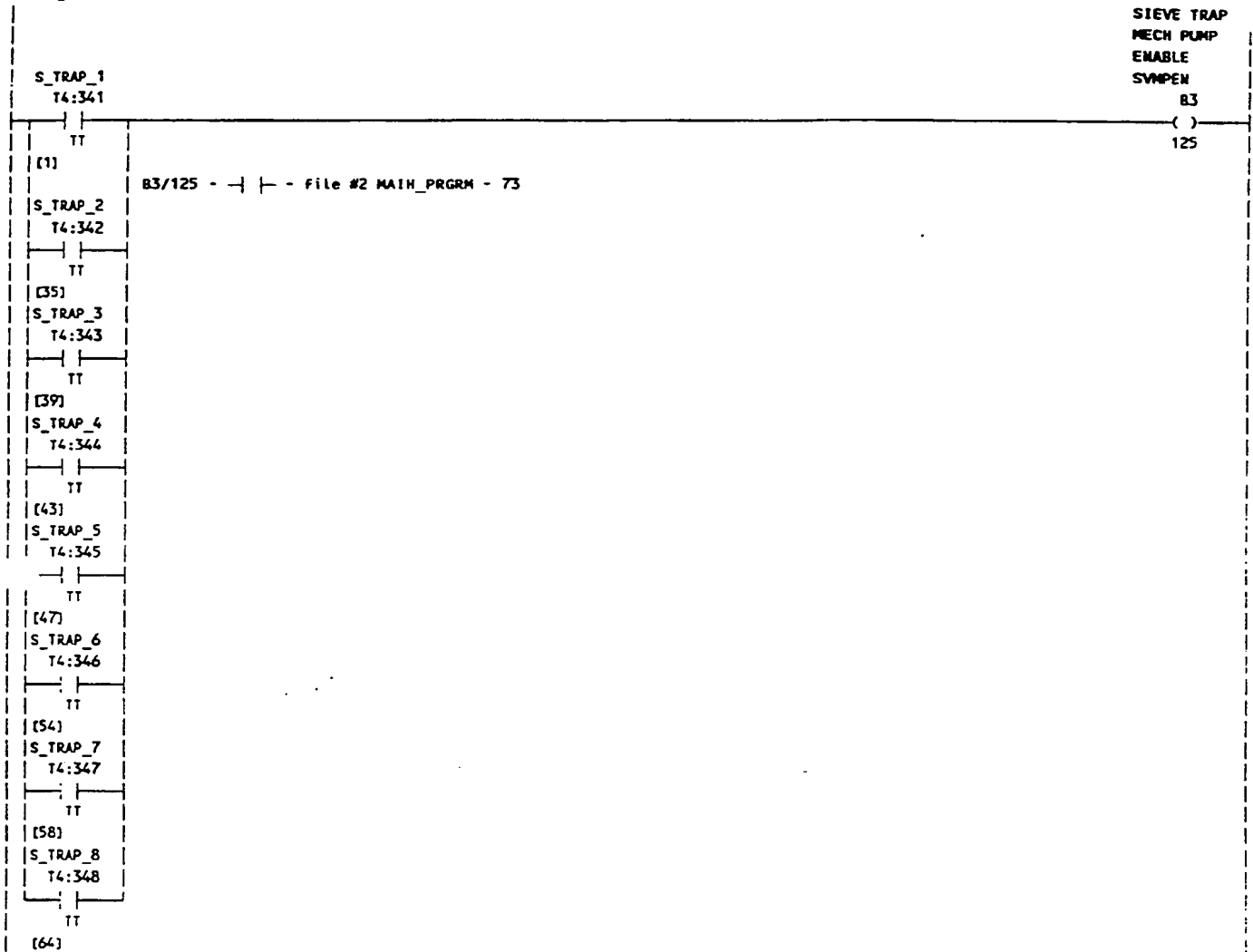
T4:130.TT - | - File #2 MAIN_PRGRM - 73

576

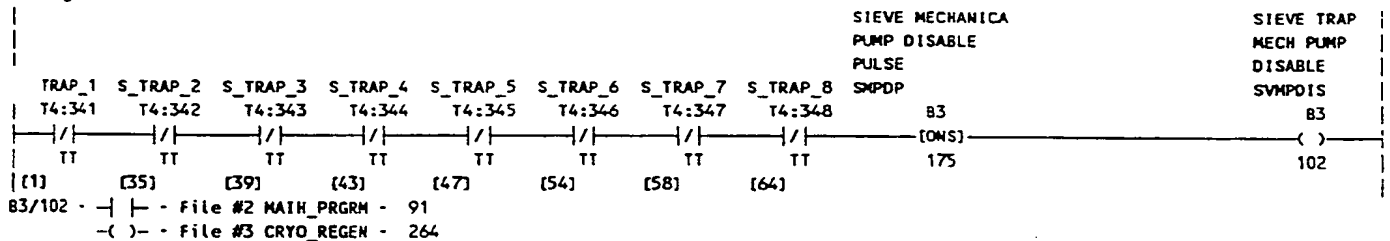
< <
MONITOR
CRYO 7
120 MIN
DONE
PGC7
T4:27
DN
[115]
PURGE TIME
MONITOR
CRYO 8
120 MIN
DONE
PGC8
T4:28
DN
[116]
>

577

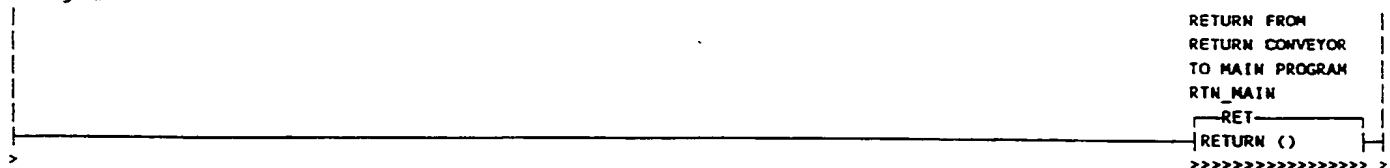
Rung #263



Rung #264



Rung #265



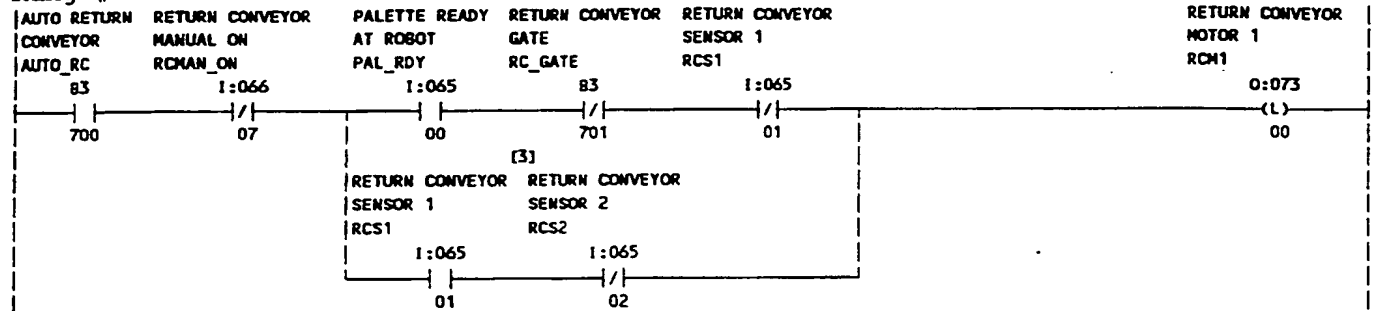
Rung #266

-----> [END] -----

579

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Rung #000



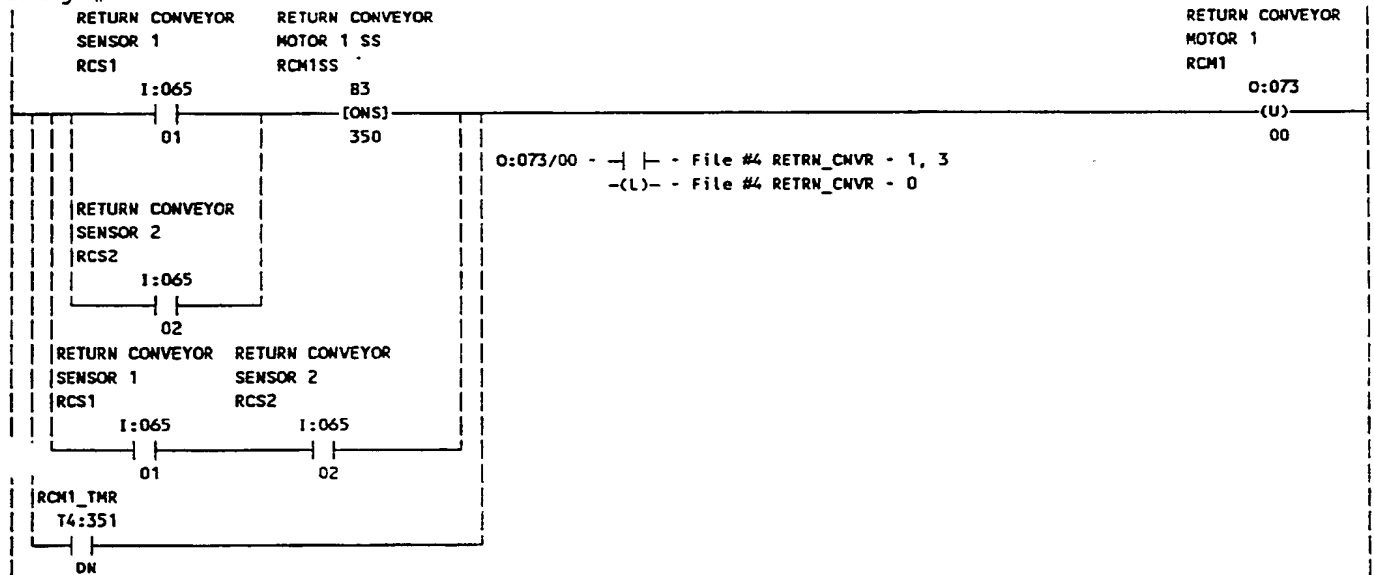
0:073/00 - | | - File #4 RETRN_CNVR - 1,3
 -(L)- - File #4 RETRN_CNVR - 0
 -(U)- - File #4 RETRN_CNVR - 2

Rung #001



T4:351.DN - | | - File #4 RETRN_CNVR - 2

Rung #002



Rung #003



580

83/701 - | | - File #4 RETRN_CNVR - 4
 -|/| - File #4 RETRN_CNVR - 0
 -(L)- File #4 RETRN_CNVR - 3
 -(U)- File #4 RETRN_CNVR - 5

Rung #004

RETURN CONVEYOR
 GATE
 RC_GATE

83
 701

[3]

RETURN CONVEYOR
 GATE TIMER
 RC_GATE_TMRA

TON	(EN)
TIMER ON DELAY	
TIMER:	T4:350
BASE (SEC):	1.0 (DN)
PRESET:	25
ACCUM:	0

T4:350.DN - | | - File #4 RETRN_CNVR - 5

Rung #005

RC_GATE_TMRA
 T4:350

DN

[4]

RETURN CONVEYOR
 GATE
 RC_GATE

83
 (U)
 701

83/701 - | | - File #4 RETRN_CNVR - 4
 -|/| - File #4 RETRN_CNVR - 0
 -(L)- File #4 RETRN_CNVR - 3
 -(U)- File #4 RETRN_CNVR - 5

Rung #006

AUTO RETURN RETURN CONVEYOR RETURN CONVEYOR
 CONVEYOR SENSOR 1 SENSOR 2
 AUTO_RC RCS1 RCS2

83 1:065 1:065
 700 01 02

0:073/01 - | | - File #4 RETRN_CNVR - 7
 -(U)- File #4 RETRN_CNVR - 8

RETURN CONVEYOR
 MOTOR 2
 RCM2

0:073
 (L)
 01

RETURN CONVEYOR RETURN CONVEYOR
 SENSOR 2 SENSOR 3
 RCS2 RCS3
 1:065 1:065
 02 03

Rung #007

RETURN CONVEYOR
 MOTOR 2
 RCM2

0:073
 01

[6]

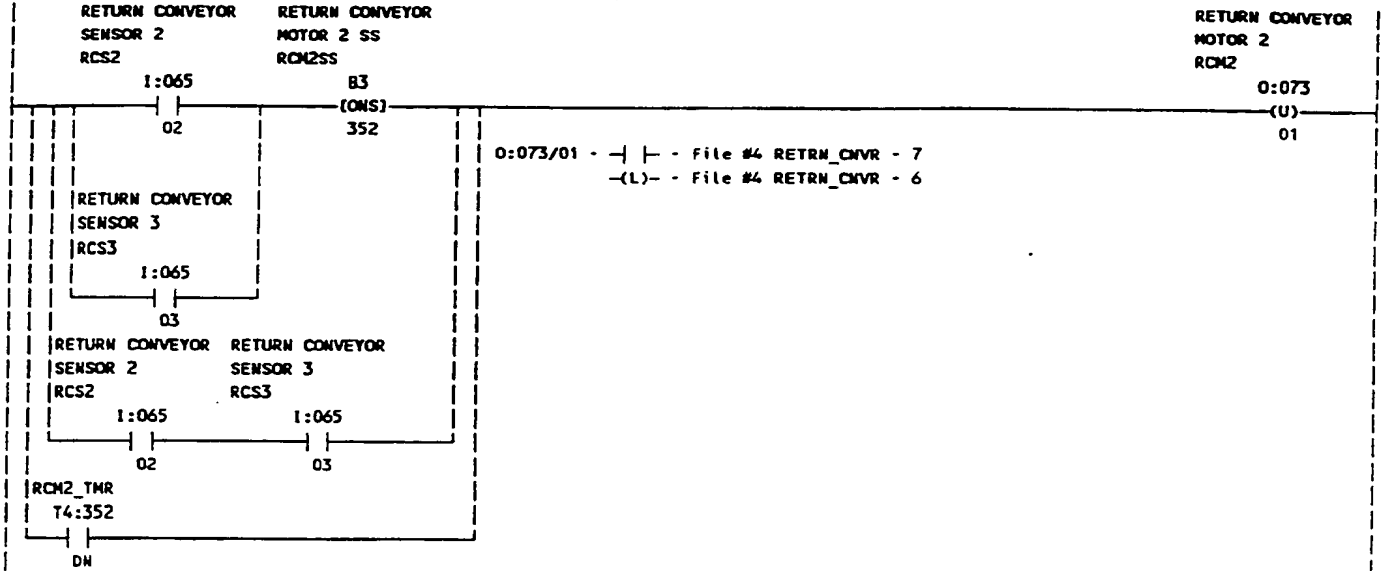
RETURN CONVEYOR
 MOTOR 2 TIMER
 RCM2_TMR

TON	(EN)
TIMER ON DELAY	
TIMER:	T4:352
BASE (SEC):	1.0 (DN)
PRESET:	25
ACCUM:	0

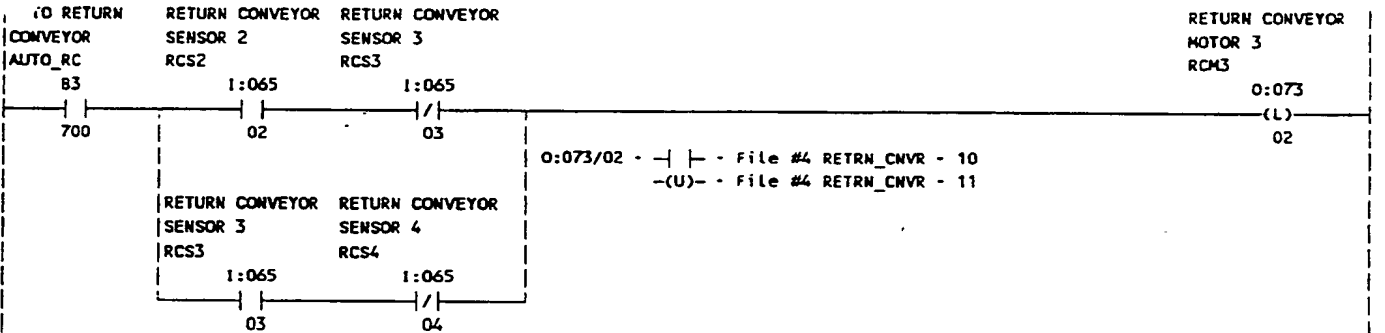
T4:352.DN - | | - File #4 RETRN_CNVR - 8

581

Rung #008



Rung #009



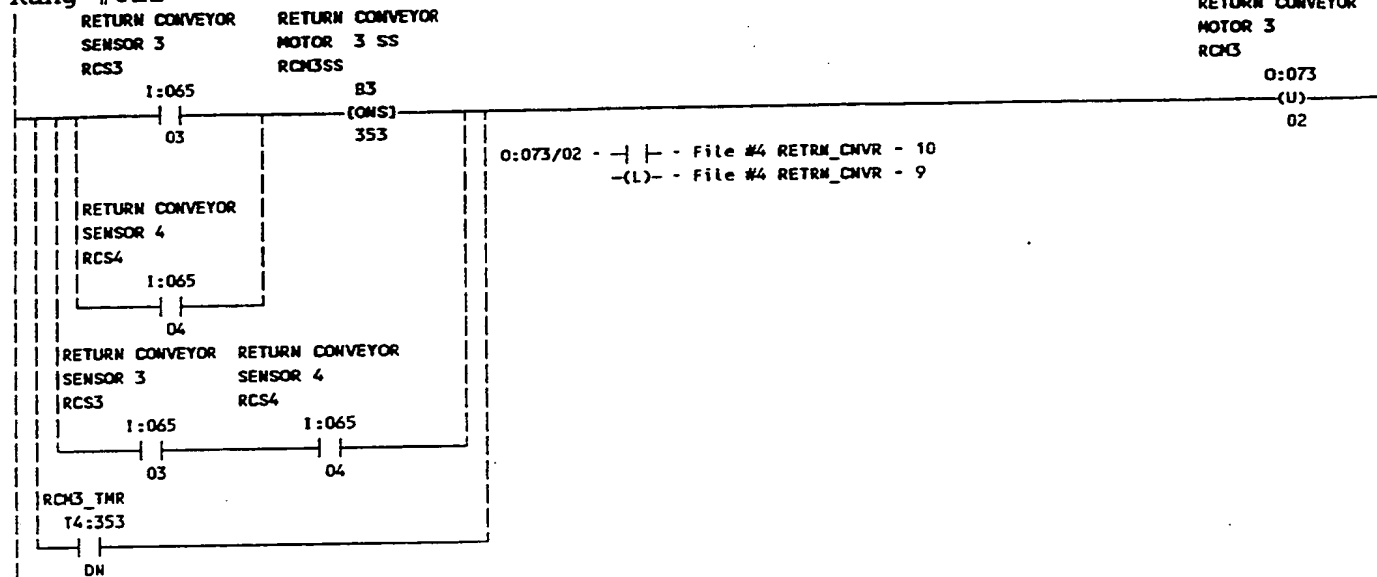
Rung #010



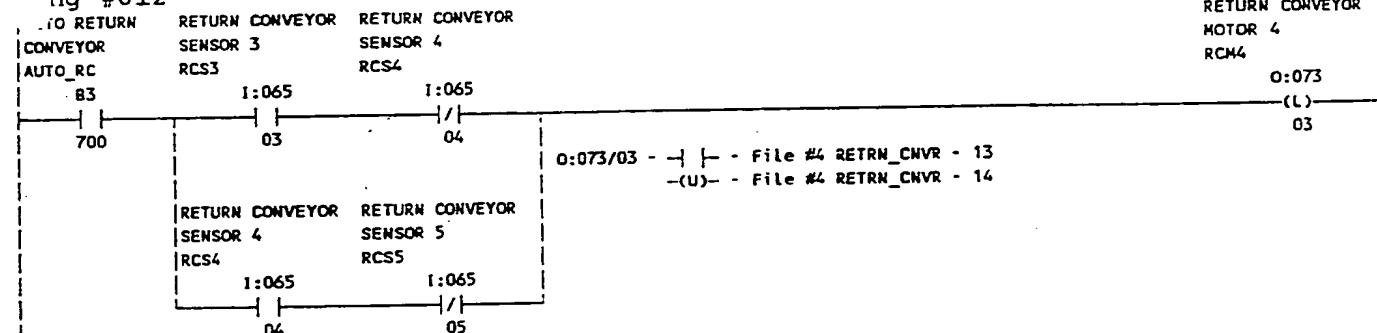
T4:353.DN - (L) - File #4 RETRN_CNVR - 11

582

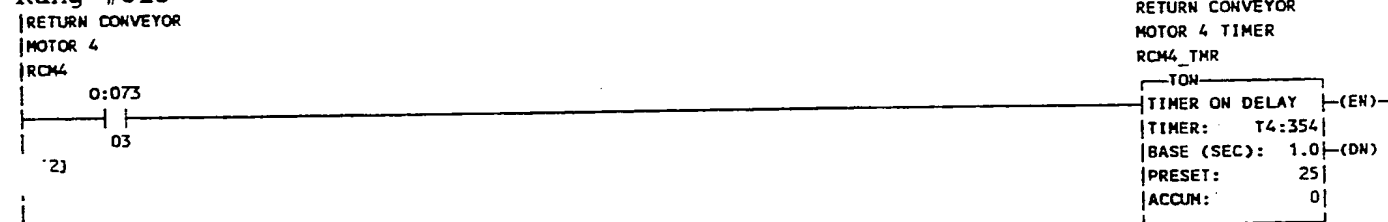
Rung #011



Rung #012



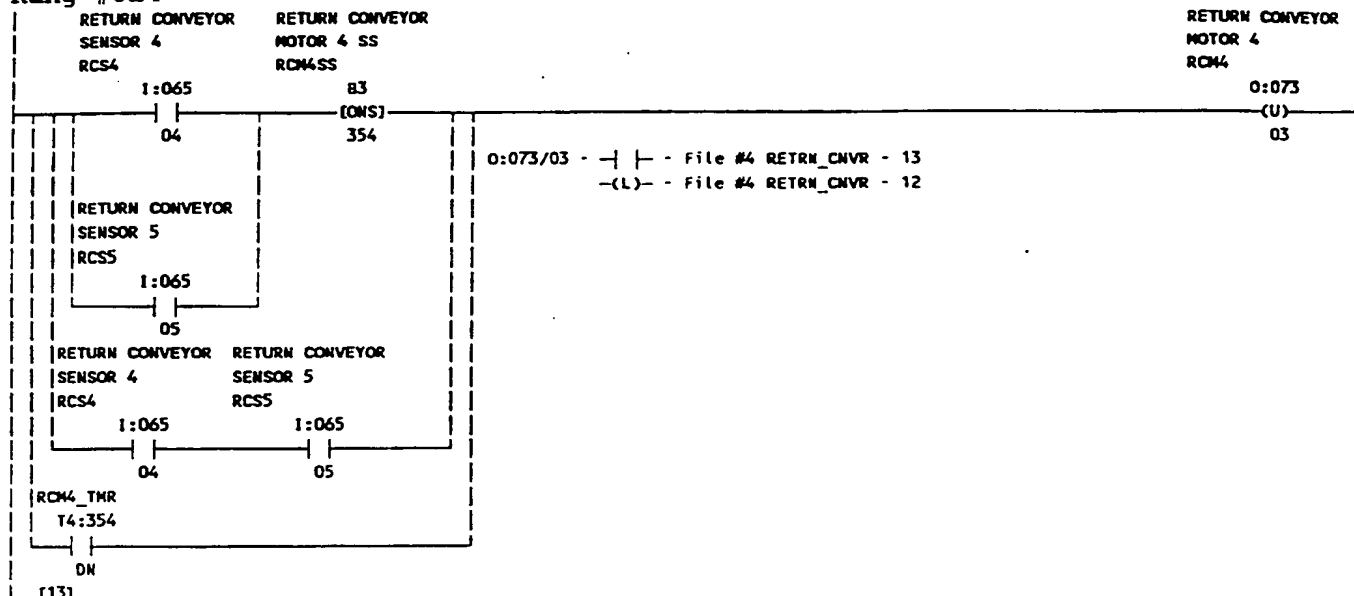
Rung #013



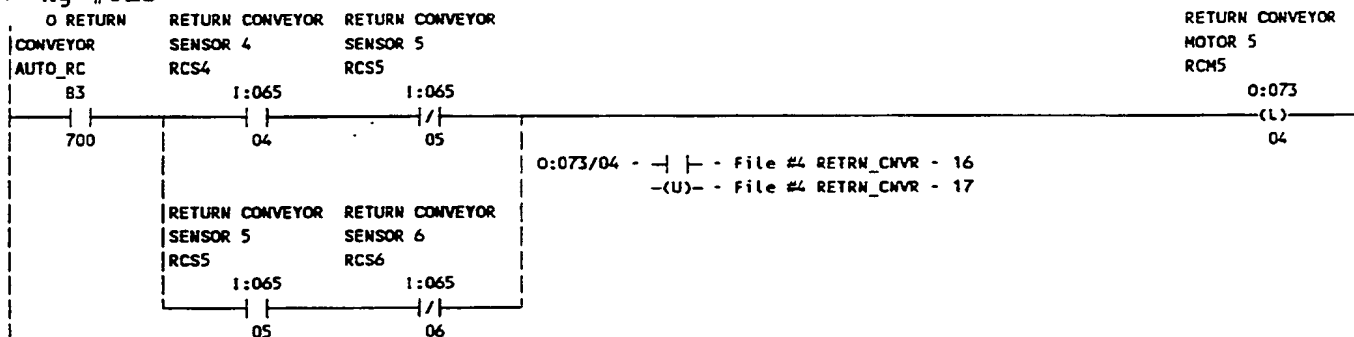
T4:354.DN - | | - File #4 RETRN_CNVR - 14

583

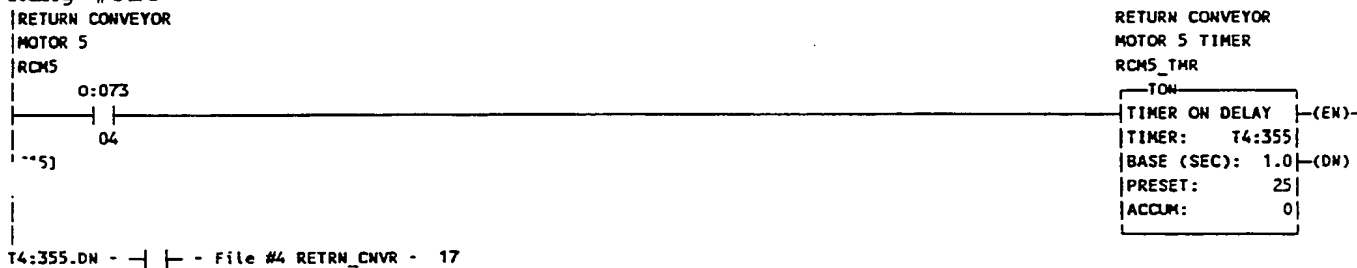
Rung #014



Rung #015

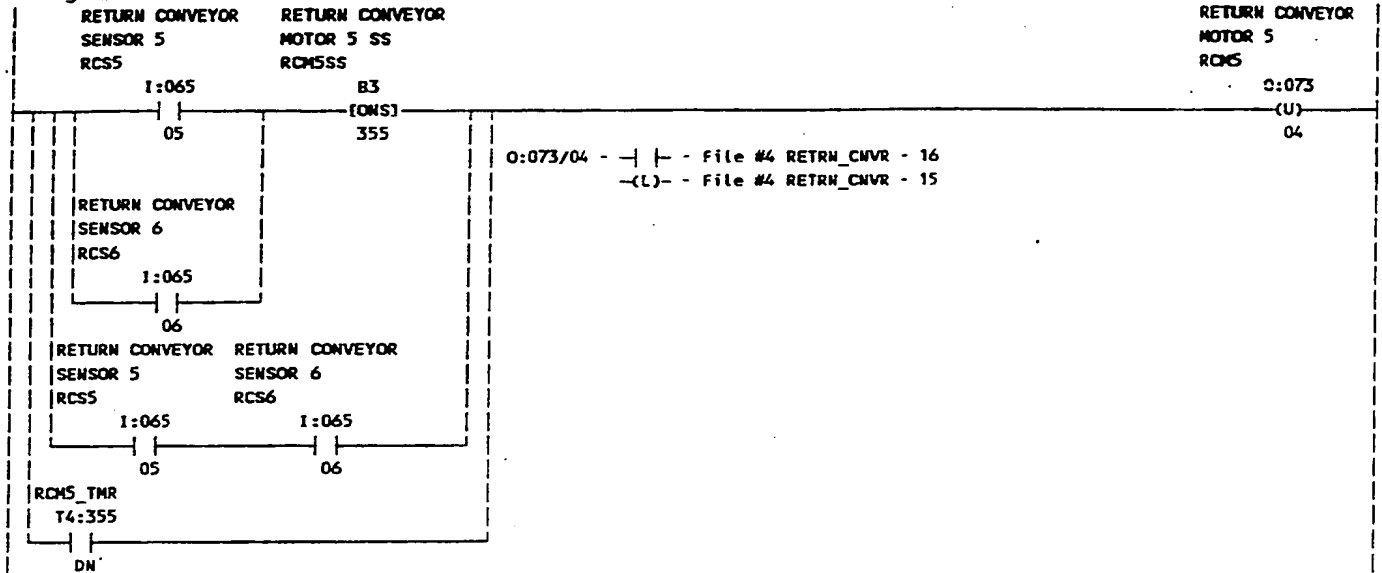


Rung #016

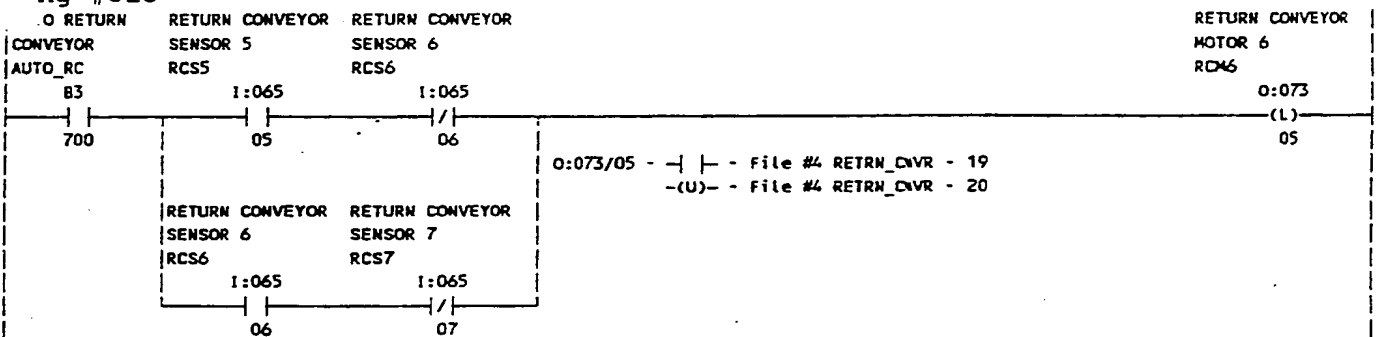


584

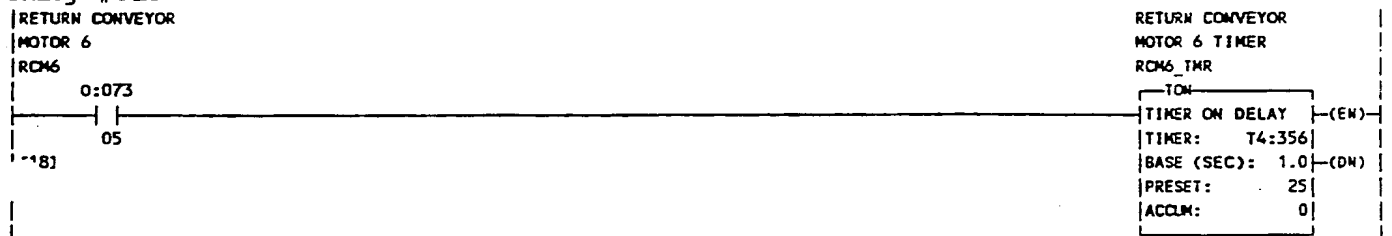
Rung #017



Rung #018



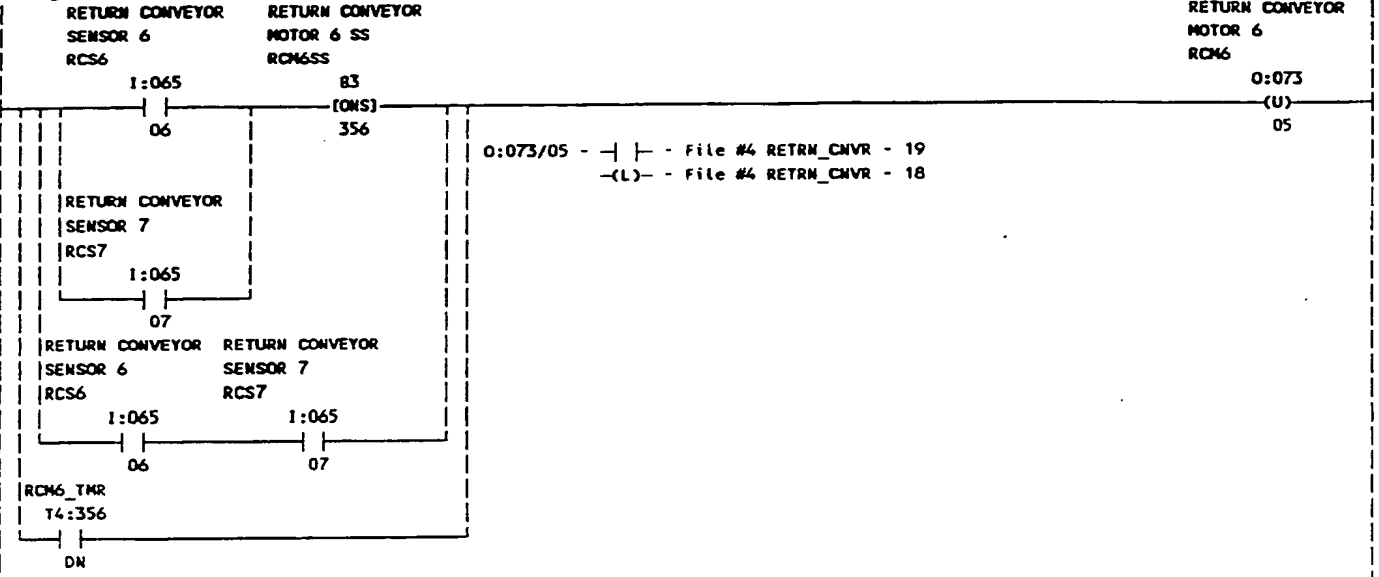
Rung #019



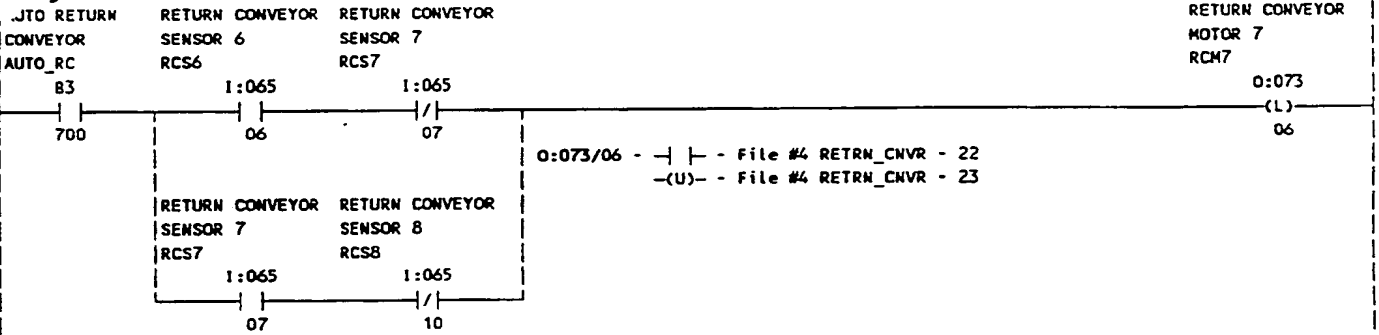
T4:356.DN - | | - File #4 RETRN_CNVR - 20

585

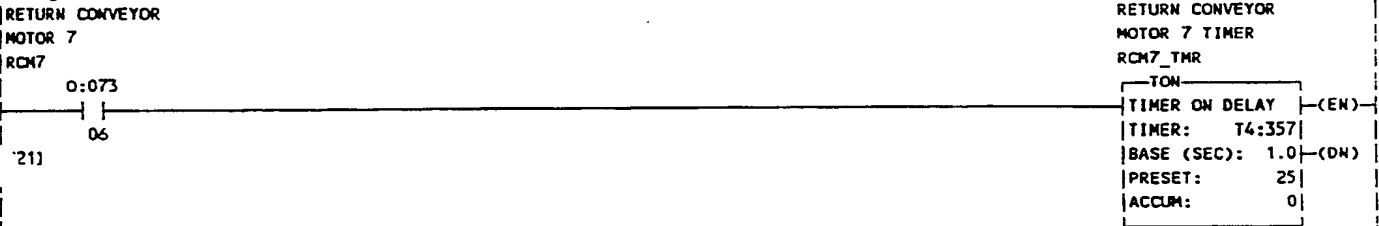
Rung #020



Rung #021



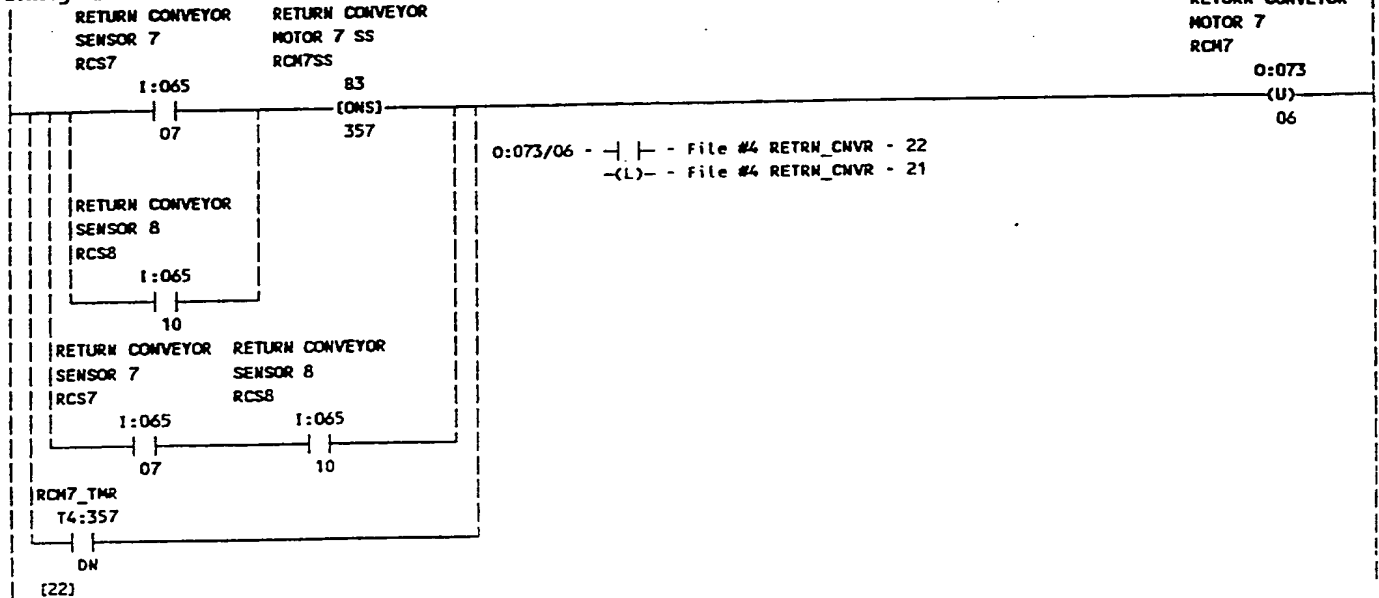
Rung #022



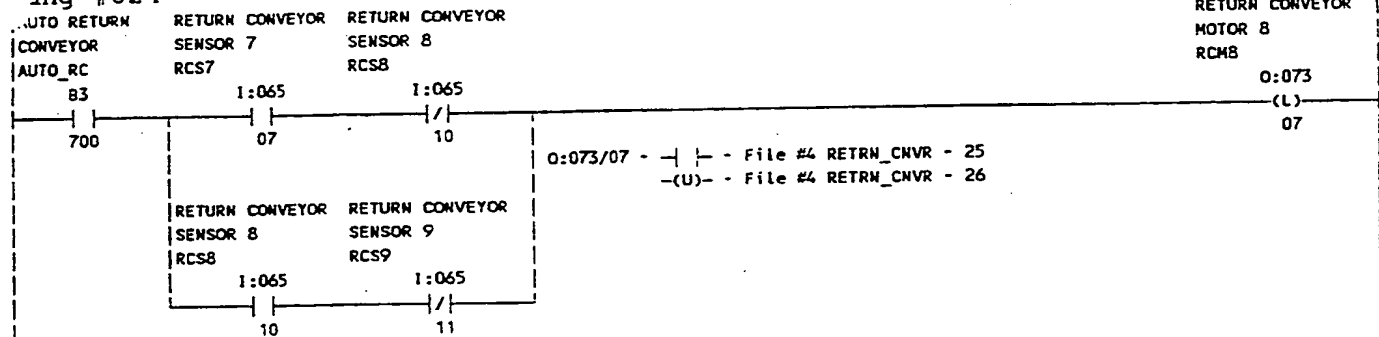
T4:357.DN - (L) - File #4 RETRN_CNVR - 23

586

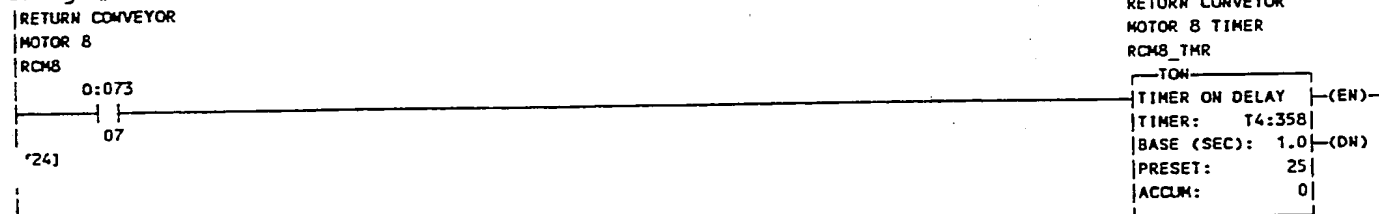
Rung #023



Rung #024



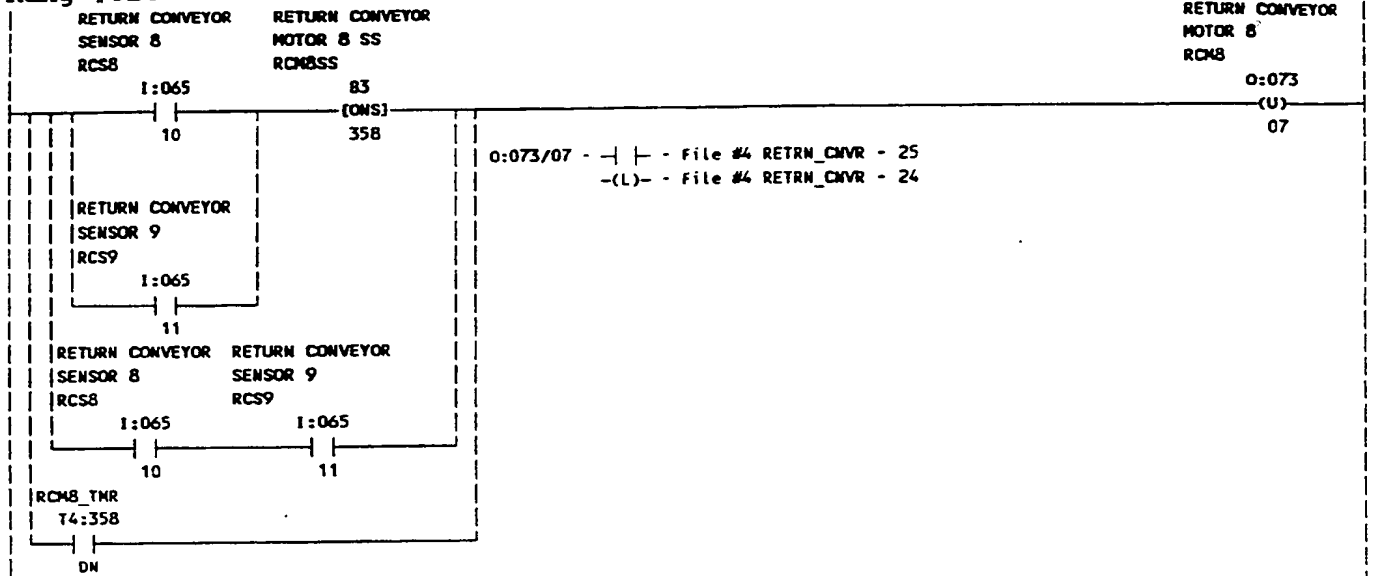
Rung #025



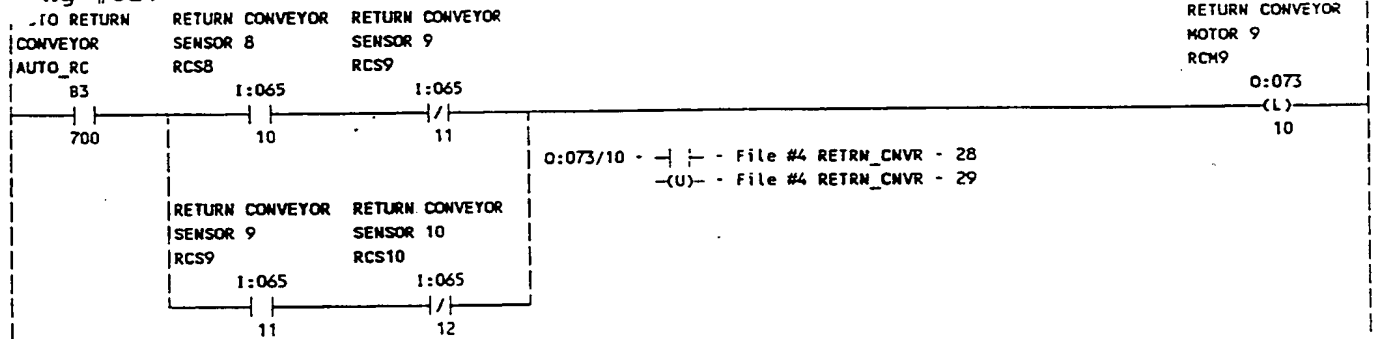
T4:358.DN - | | - File #4 RETRN_CNVR - 26

587

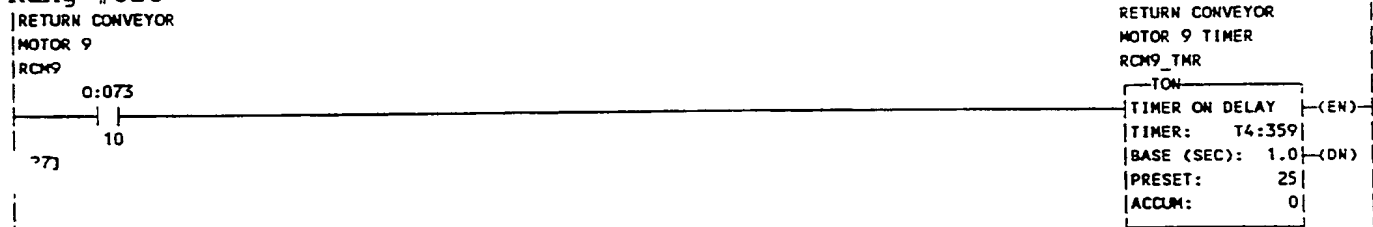
Rung #026



Rung #027



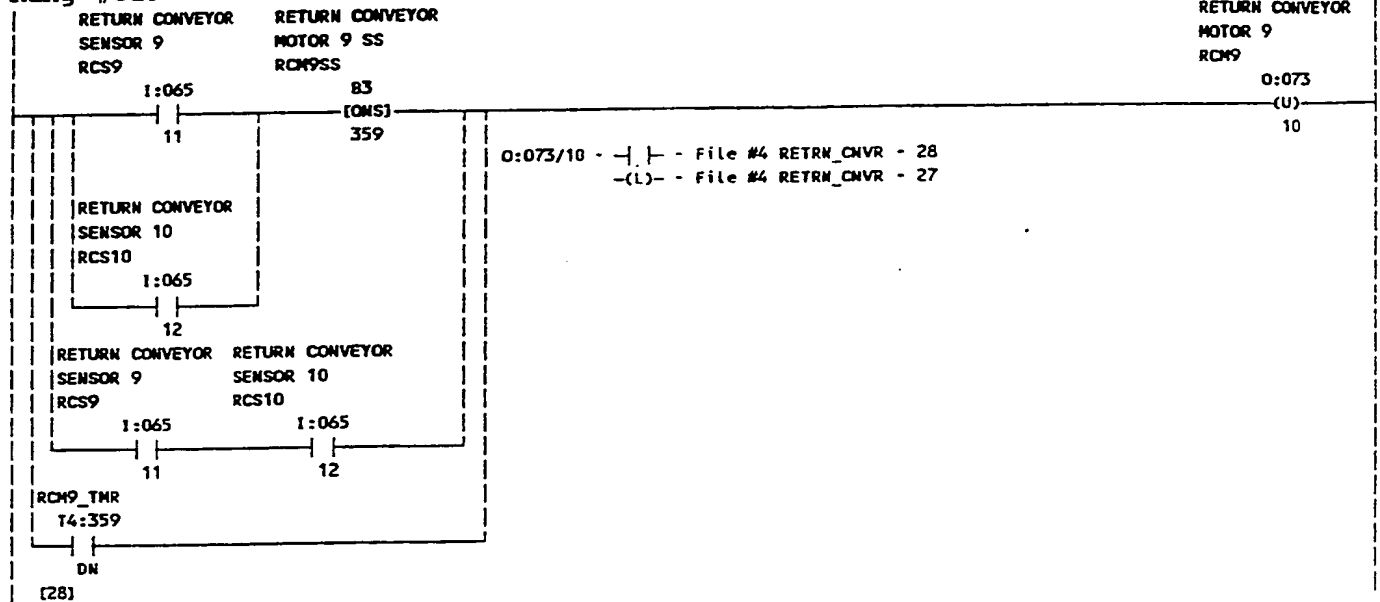
Rung #028



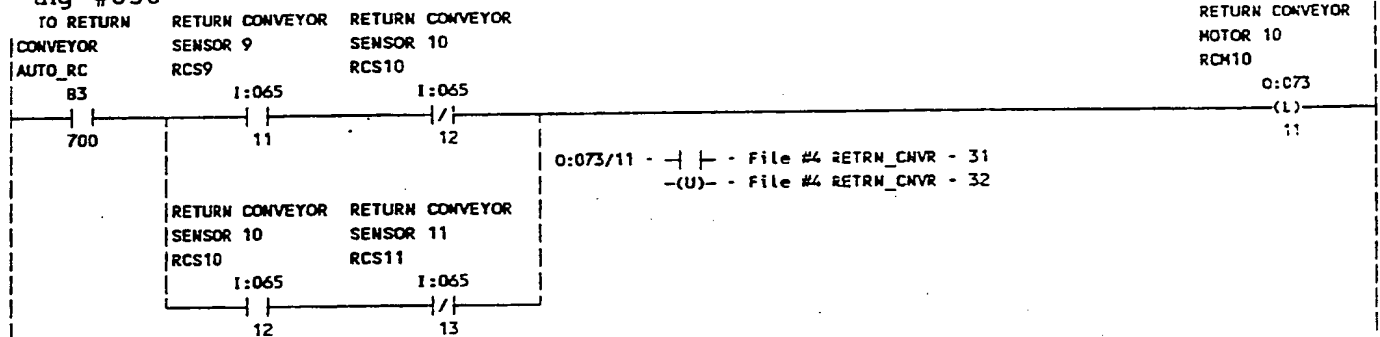
T4:359.DN - | | - File #4 RETRN_CMVR - 29

588

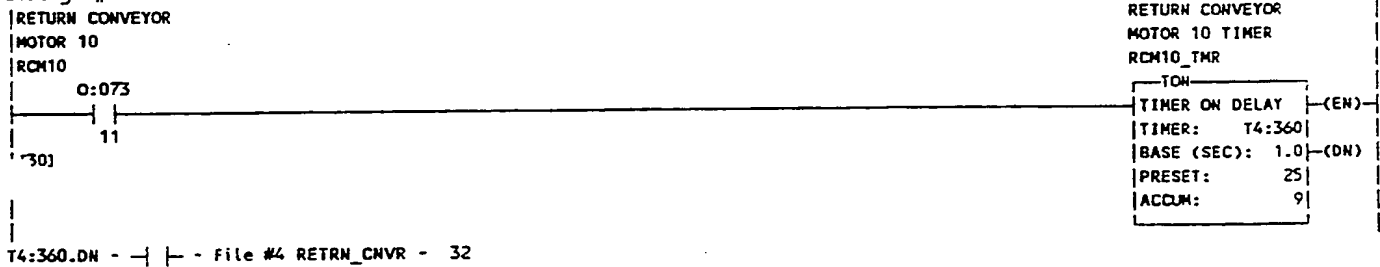
Rung #029



Rung #030

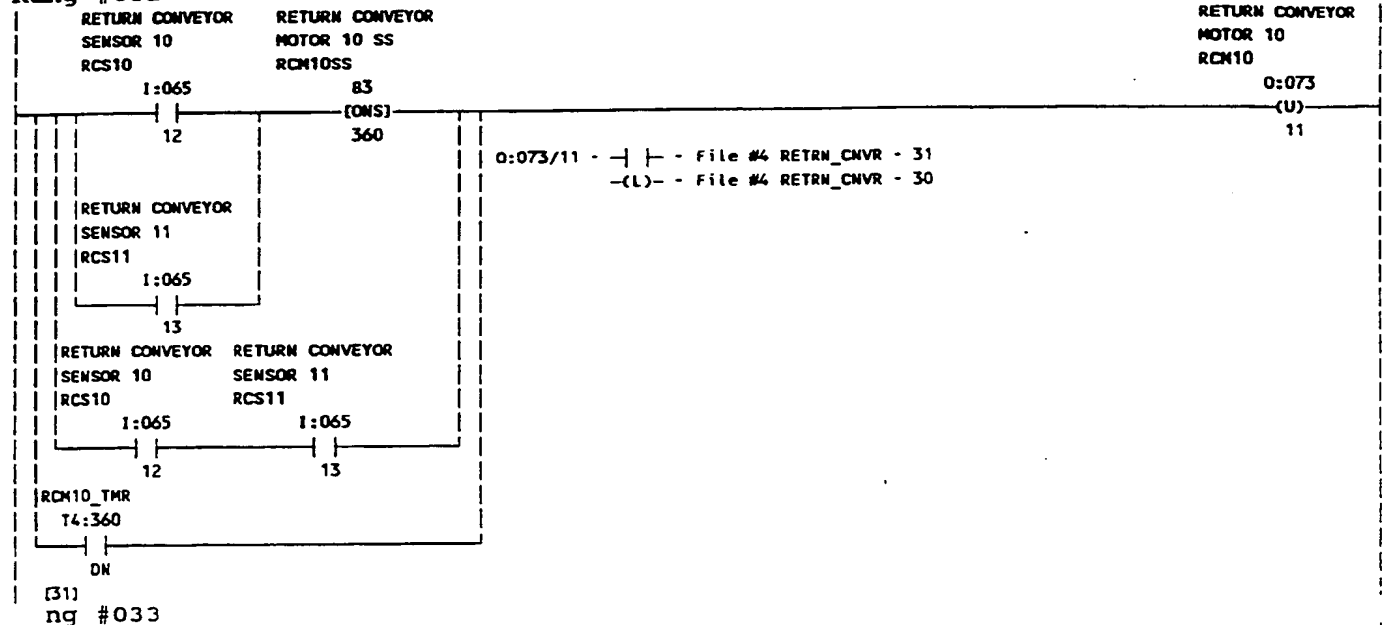


Rung #031

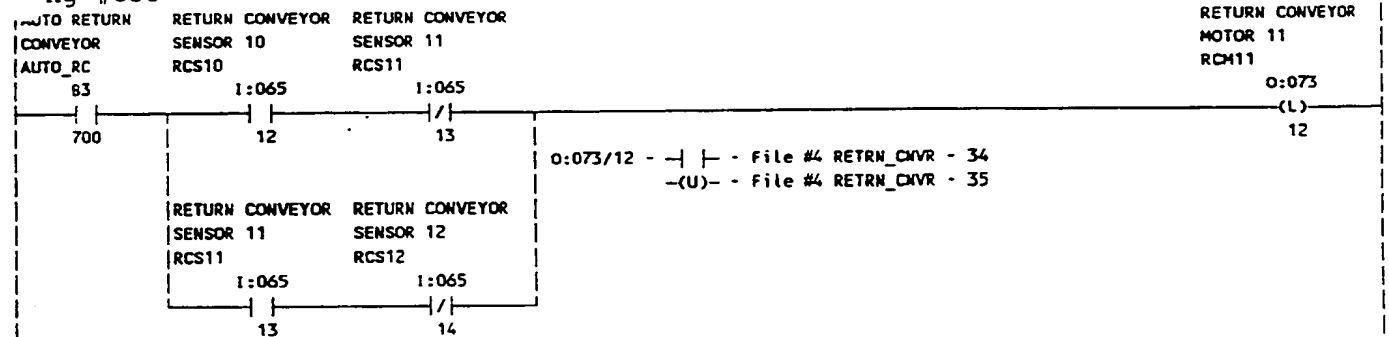


589

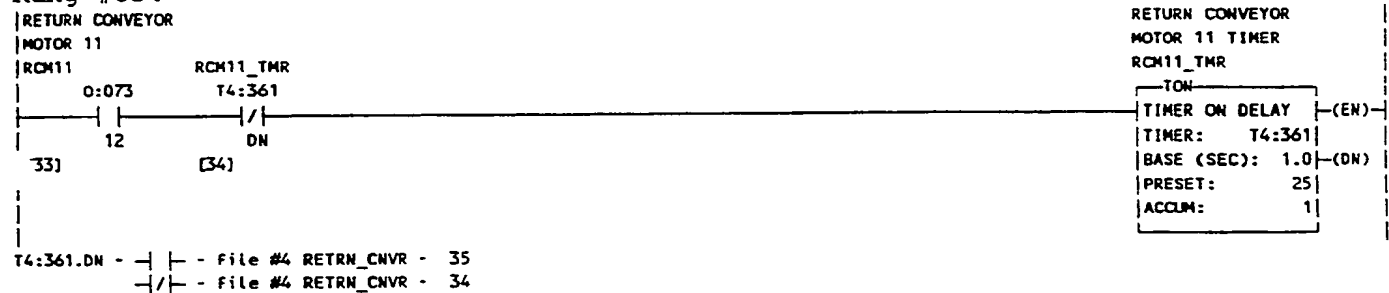
Rung #032



Rung #033

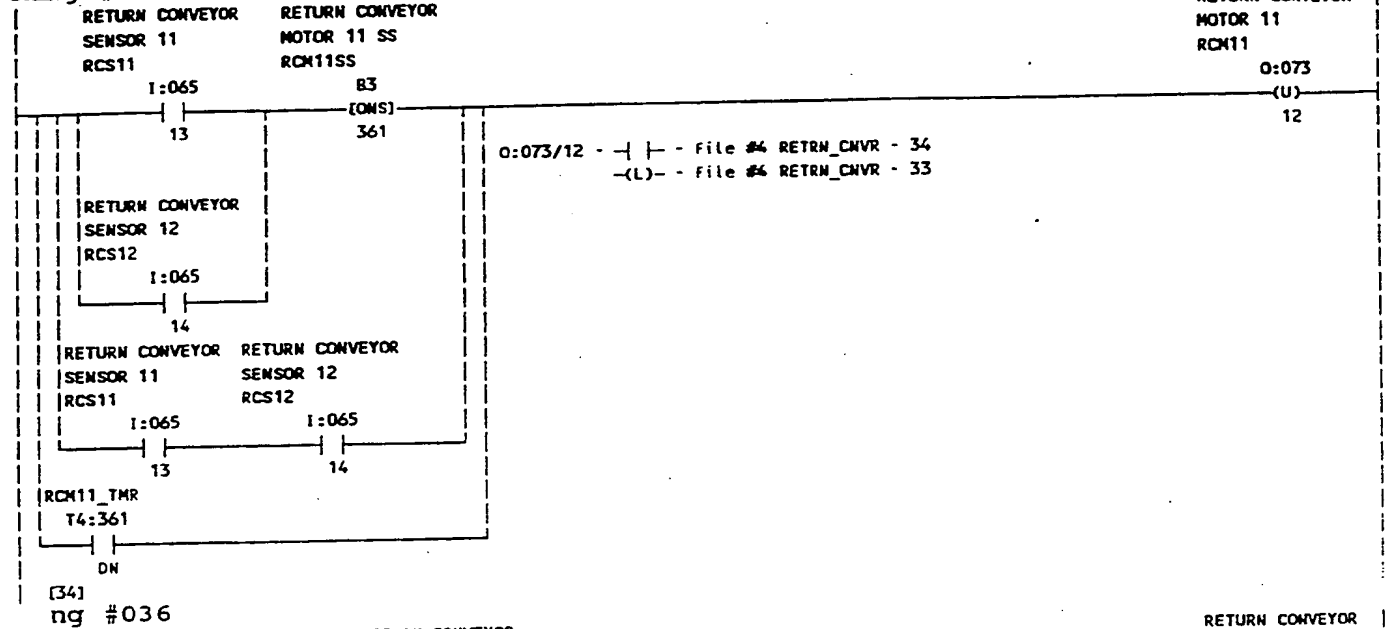


Rung #034

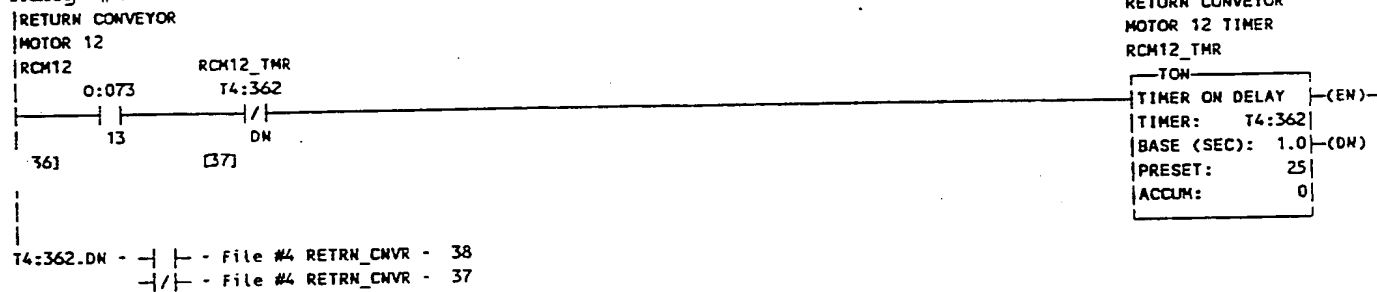


590

Rung #035

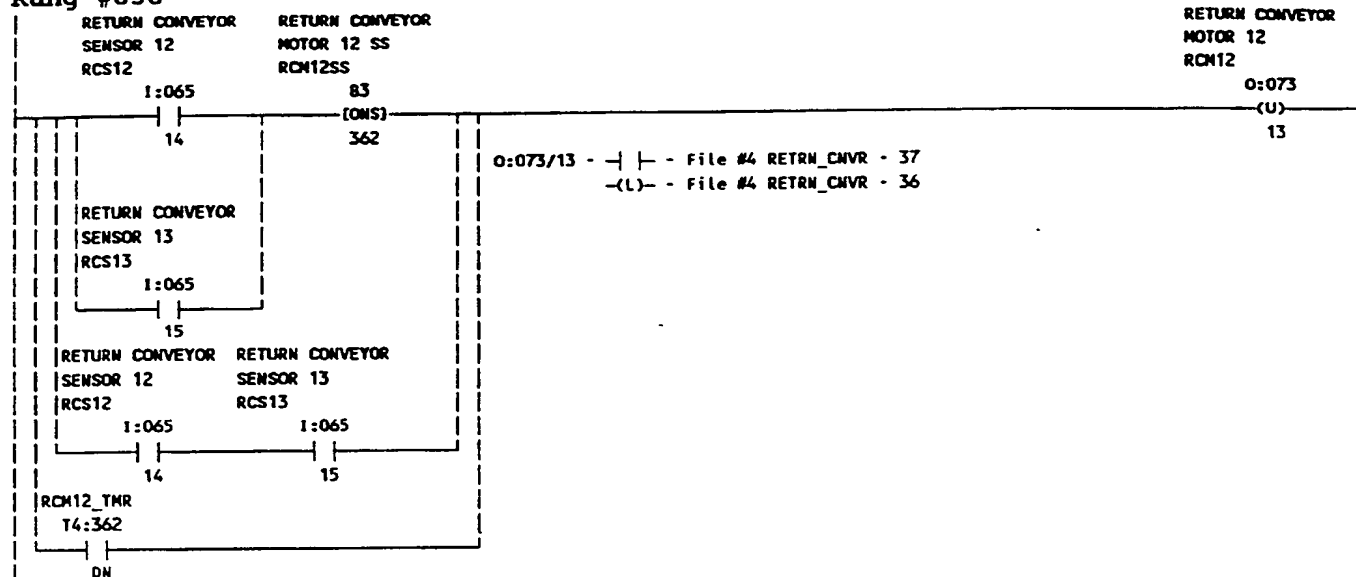


Rung #037



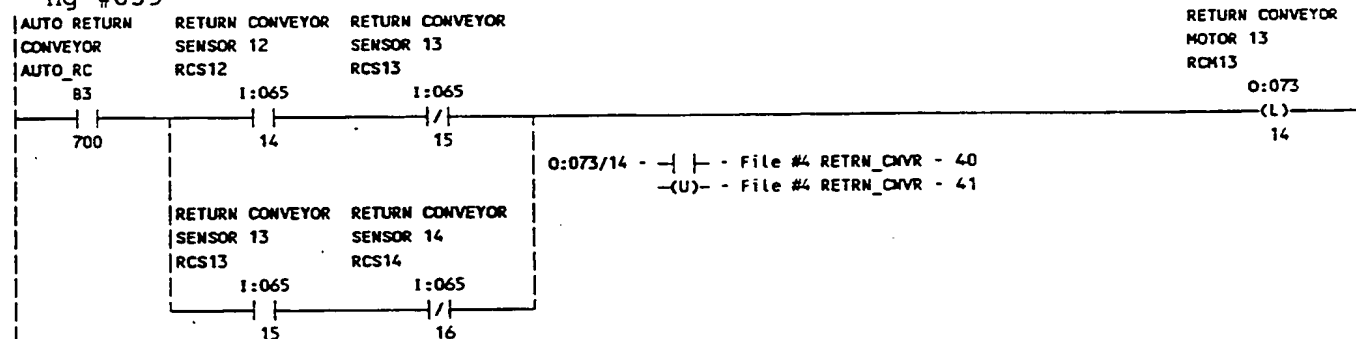
591

Rung #038

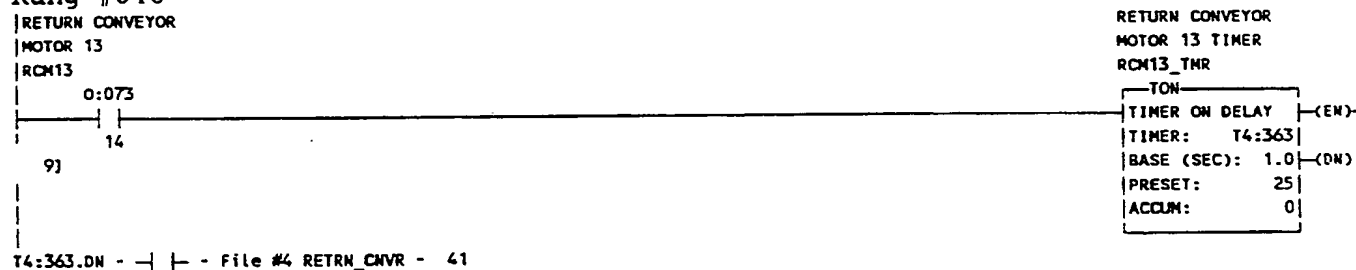


(37)

Rung #039

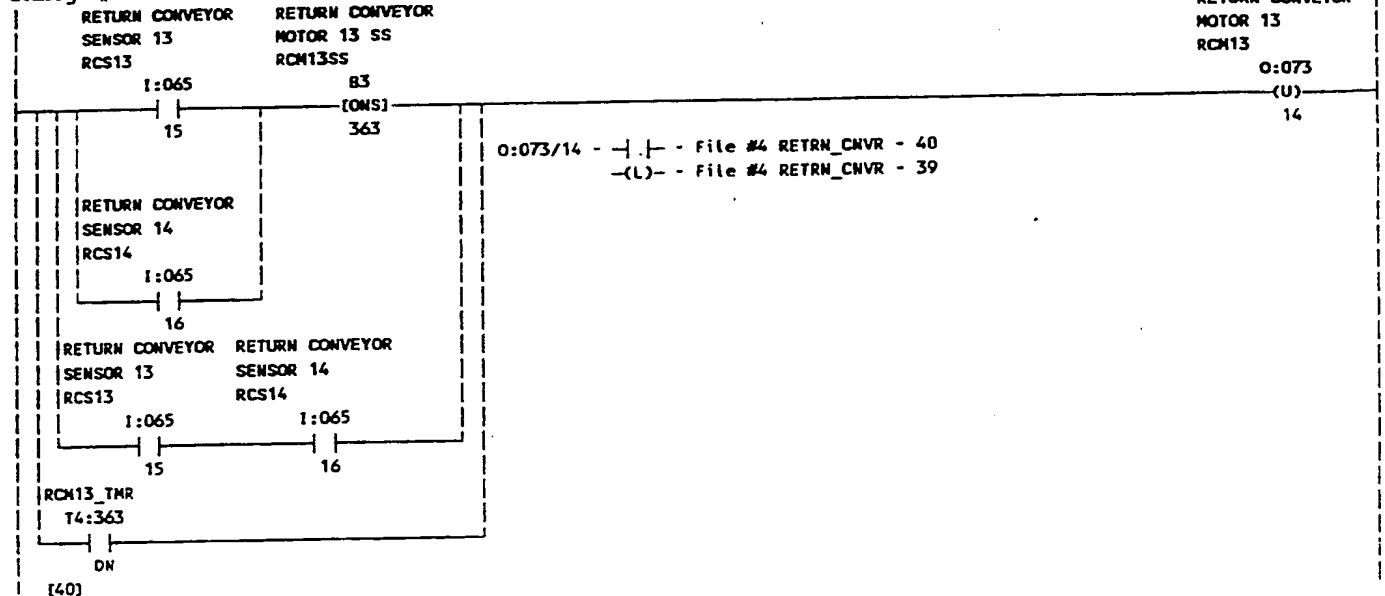


Rung #040

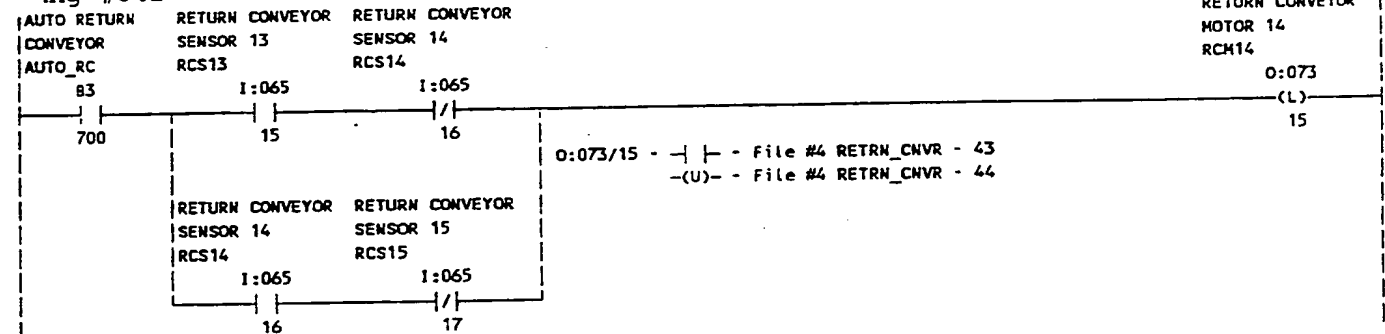


592

Rung #041



Rung #042



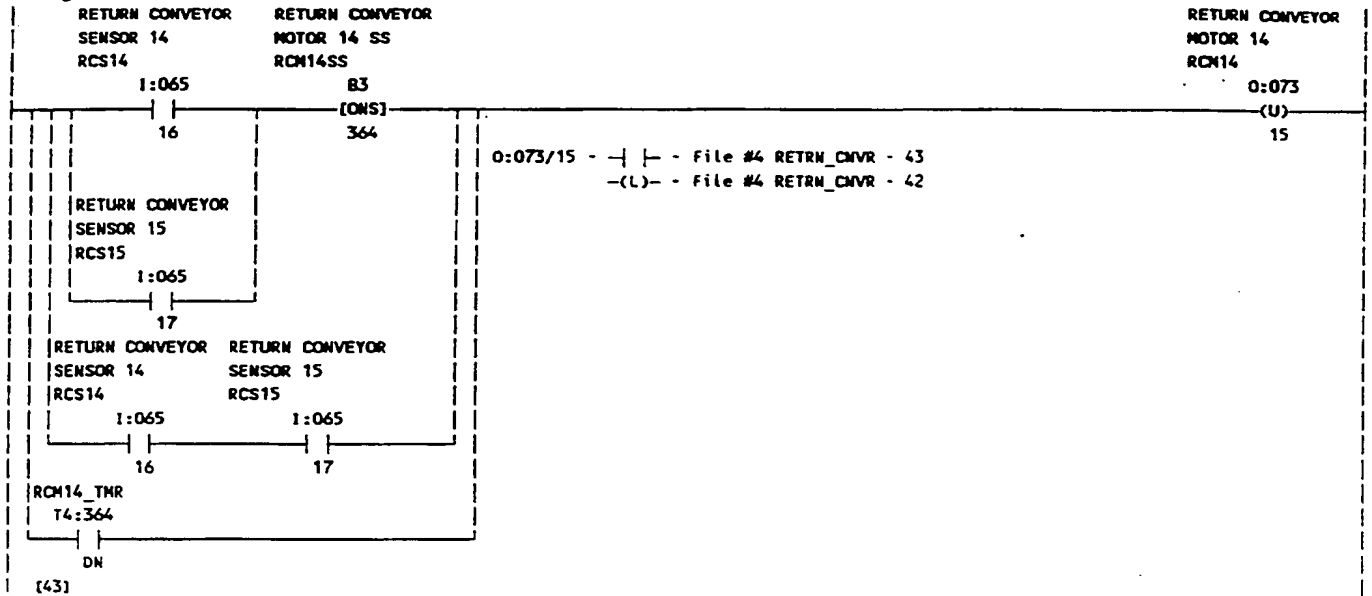
Rung #043



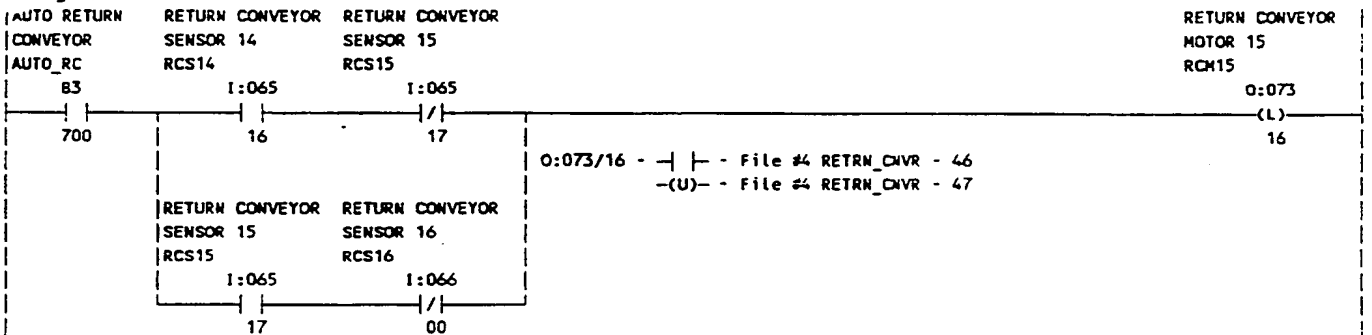
T4:364.DN - | | - File #4 RETRN_CNVR - 44

593

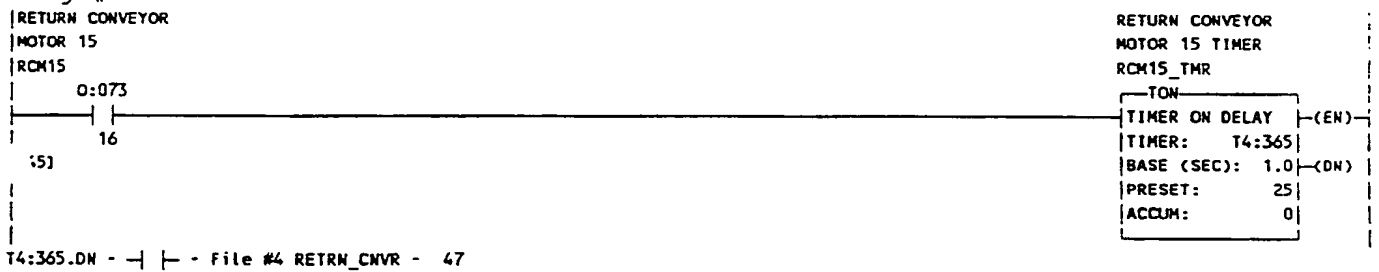
Rung #044



Rung #045

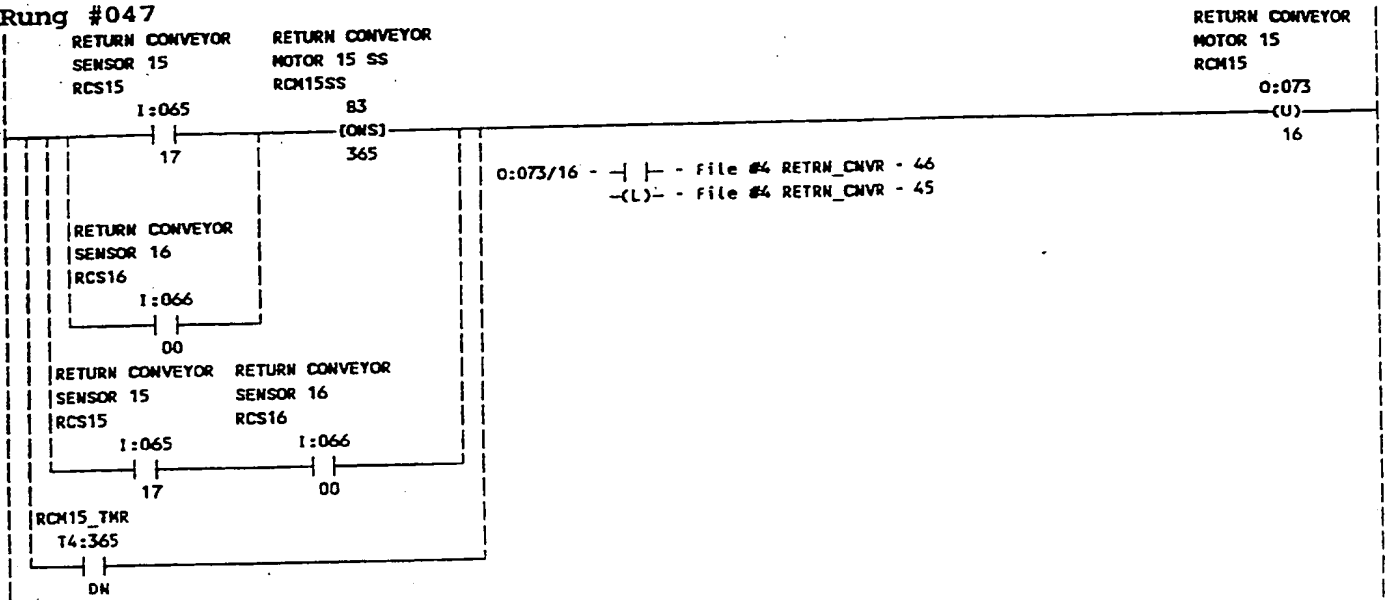


Rung #046



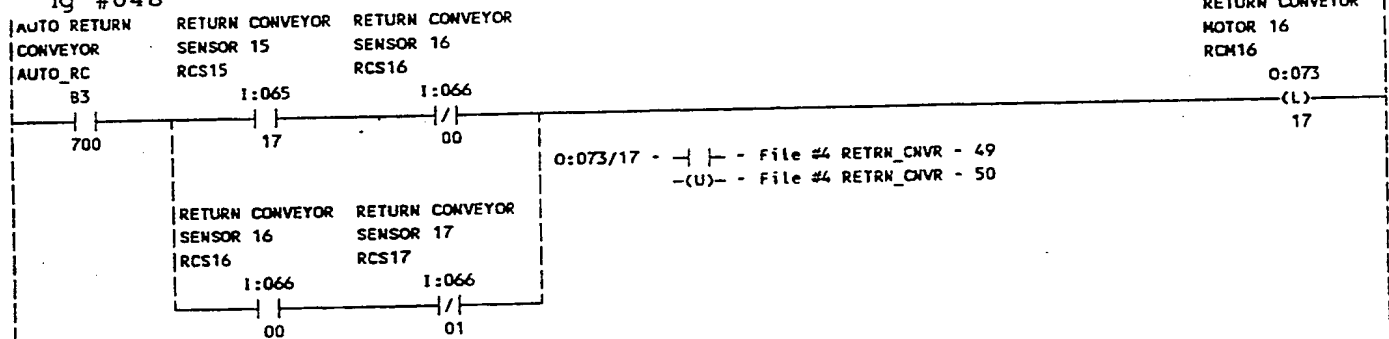
594

Rung #047

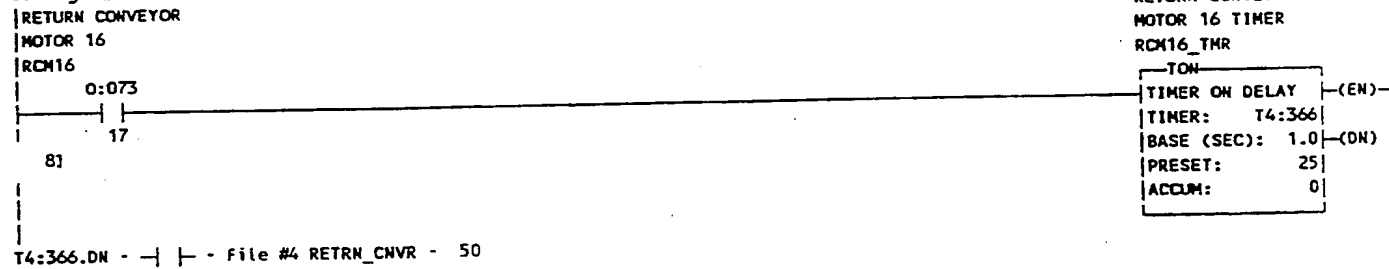


[46]

Rung #048

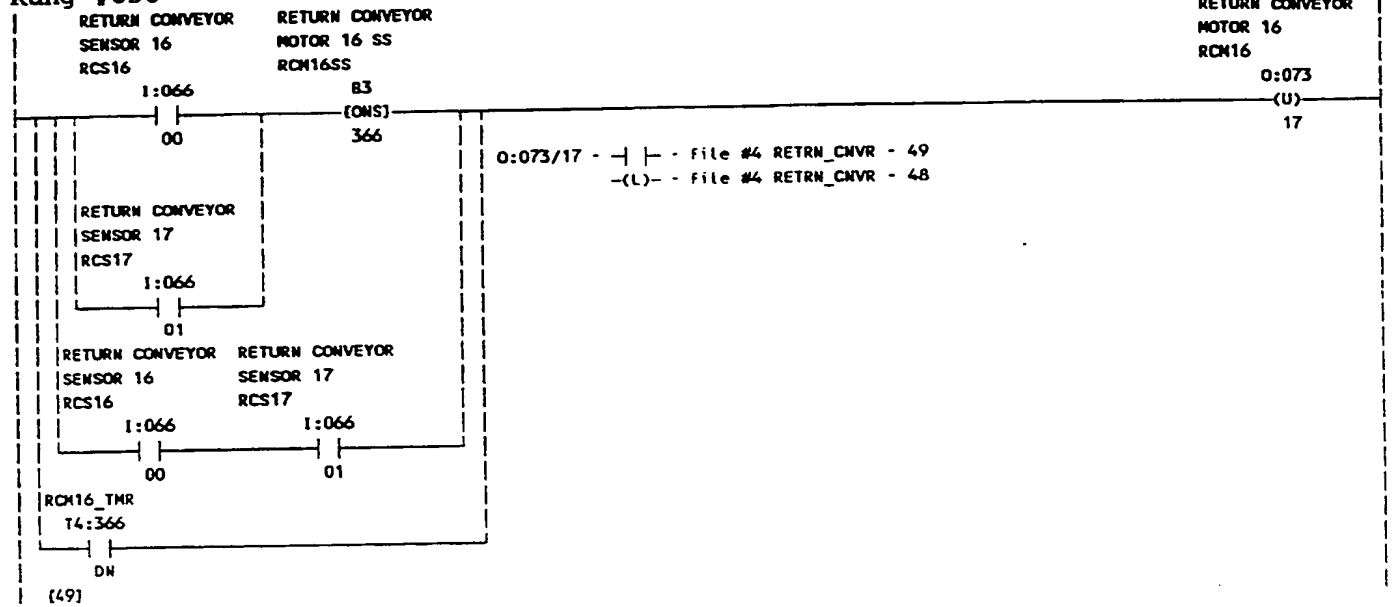


Rung #049

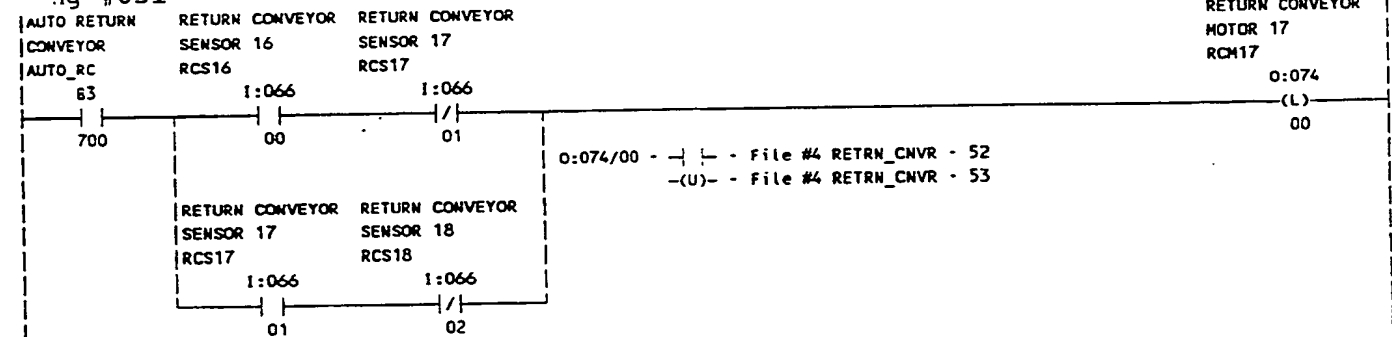


595

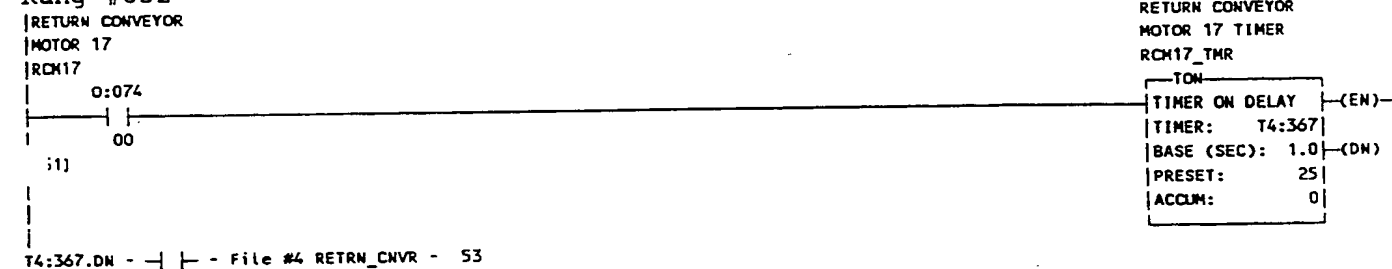
Rung #050



Rung #051

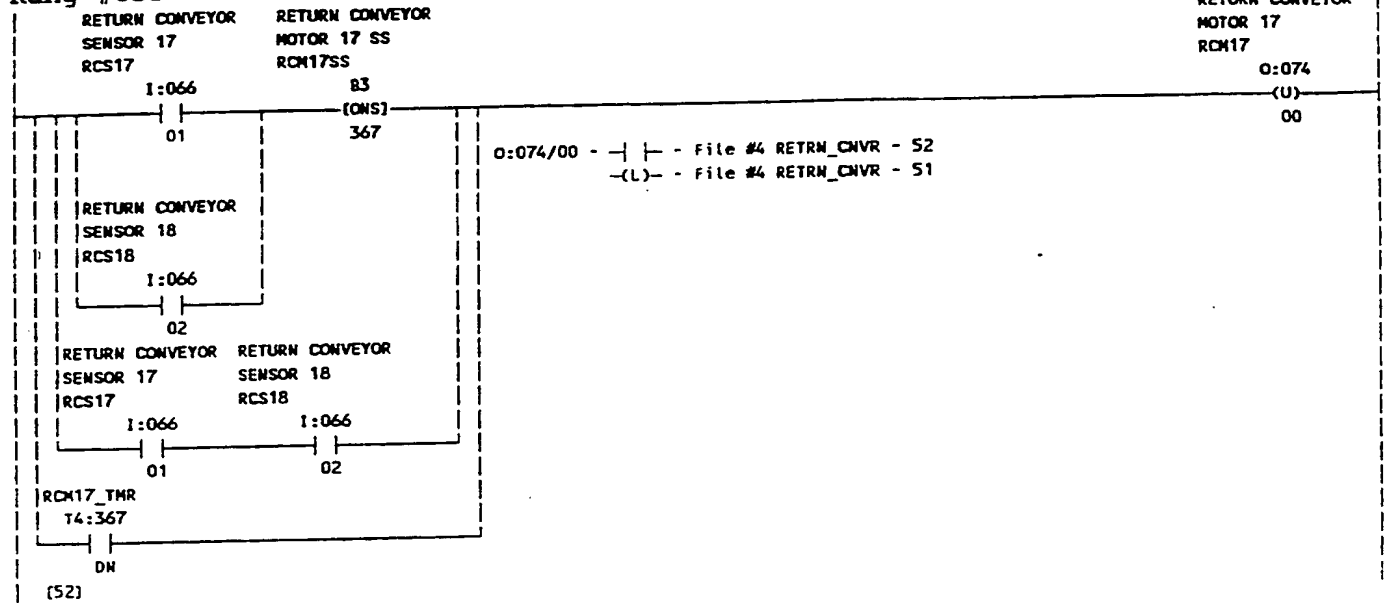


Rung #052

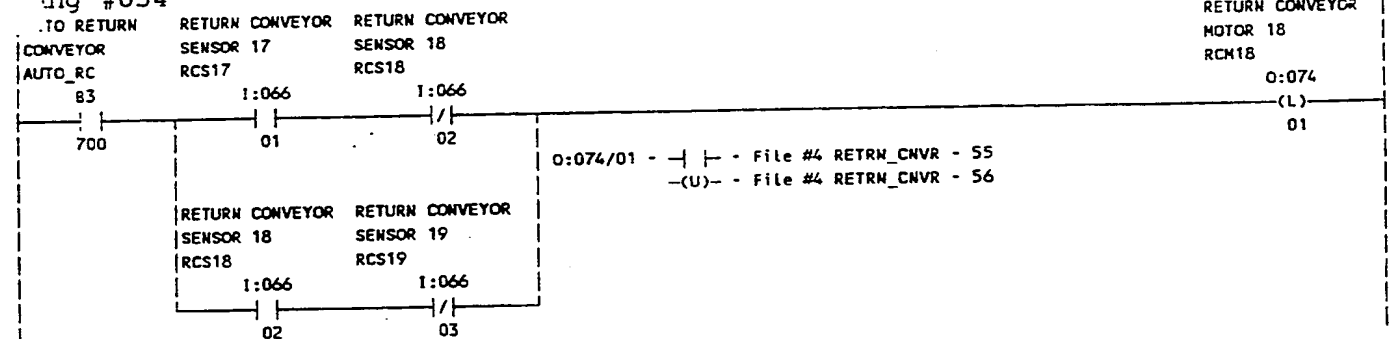


596

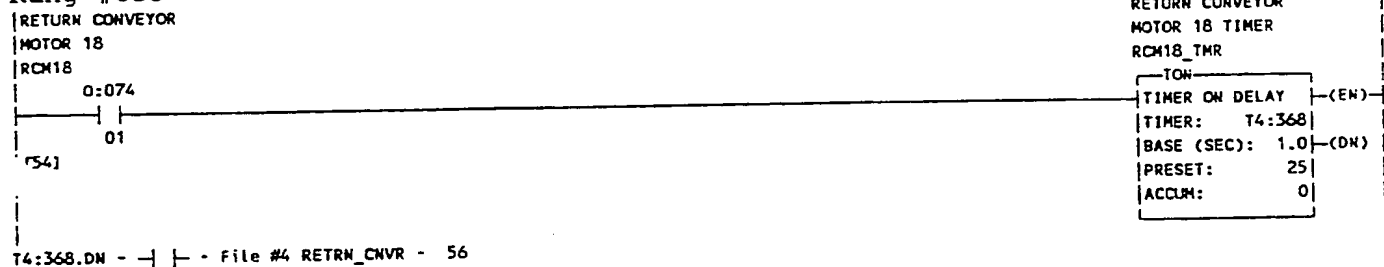
Rung #053



Rung #054

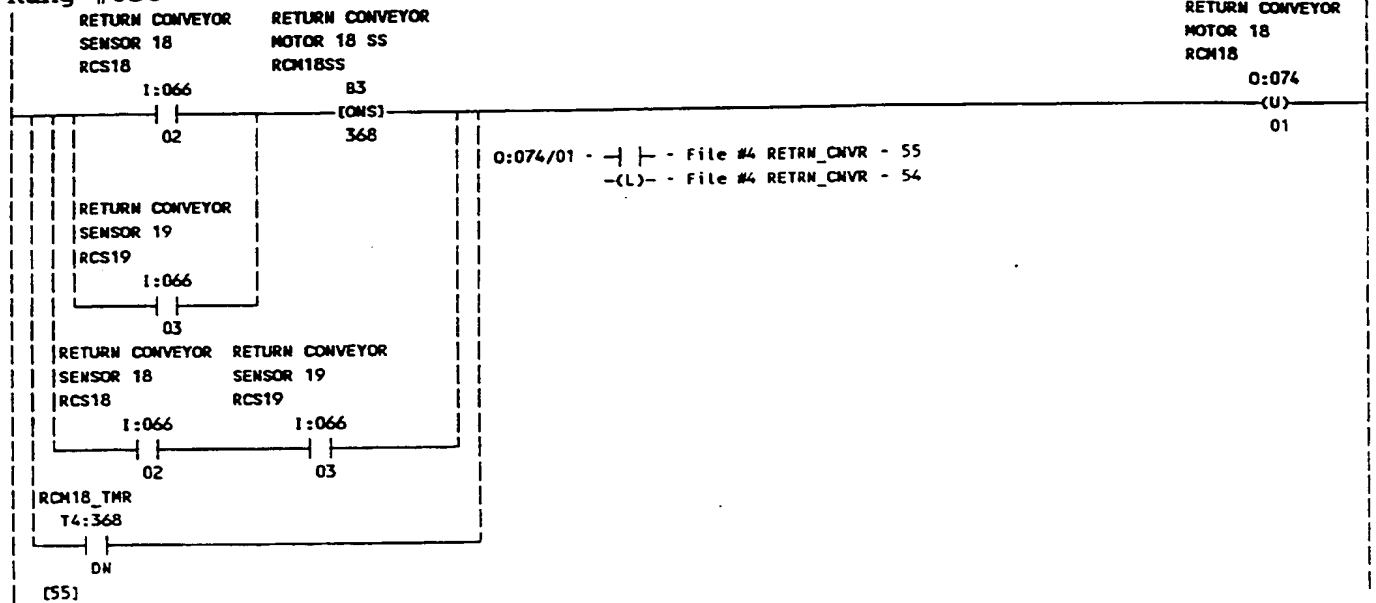


Rung #055

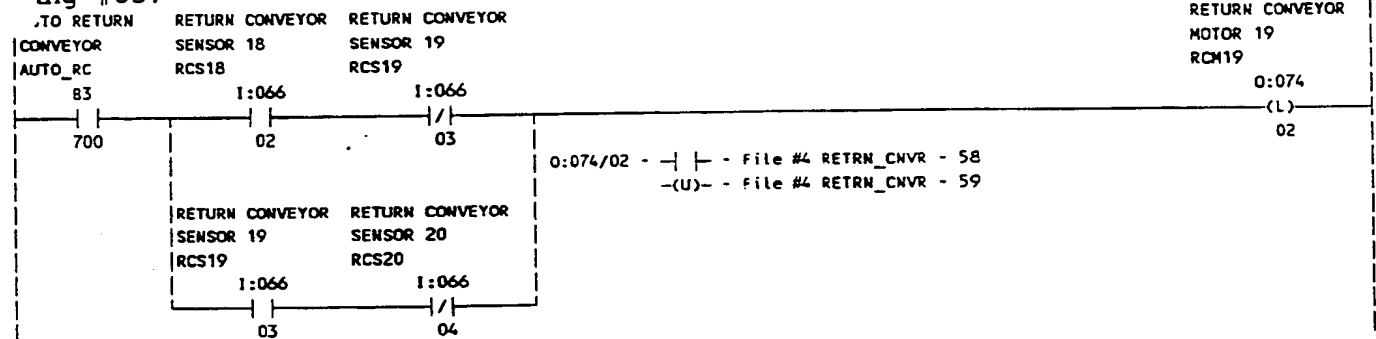


597

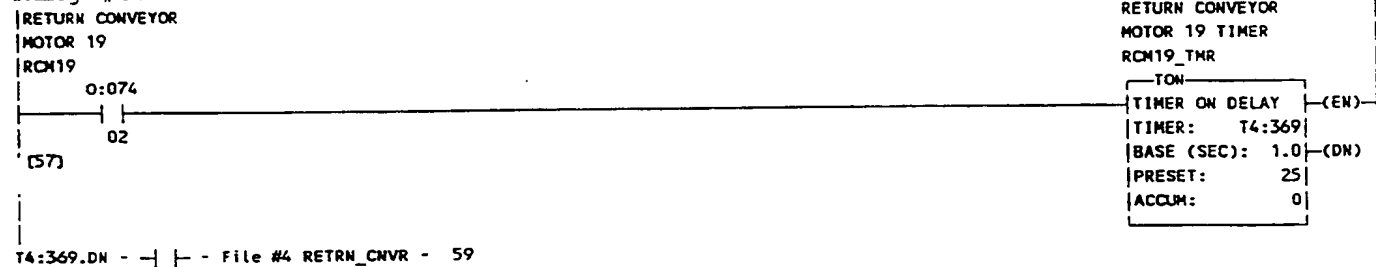
Rung #056



Rung #057

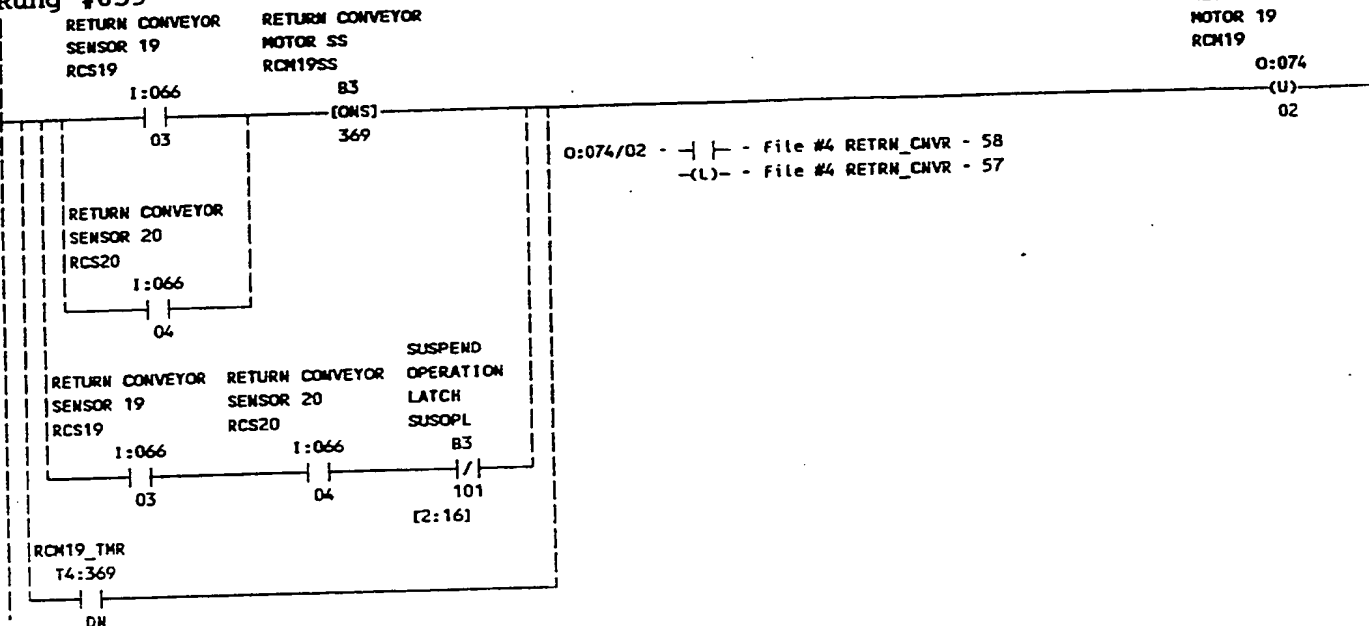


Rung #058

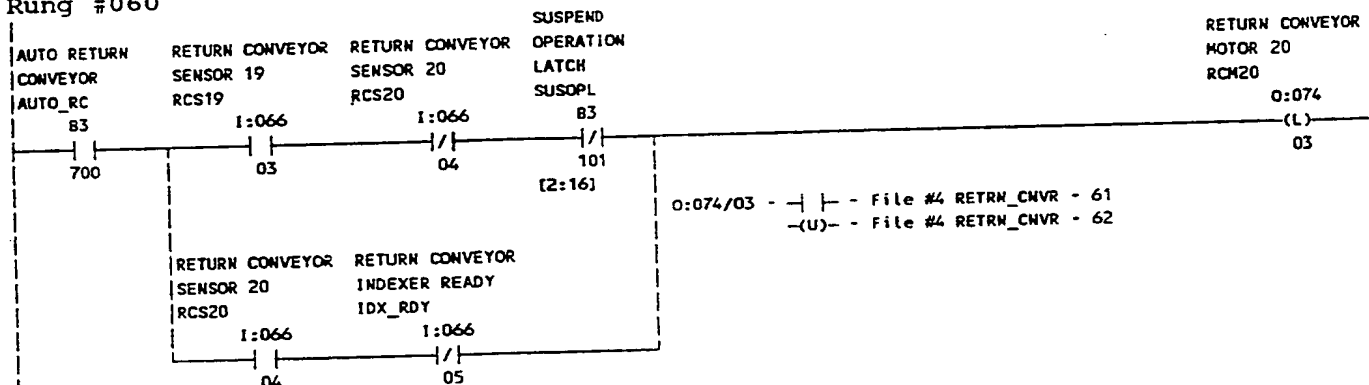


598

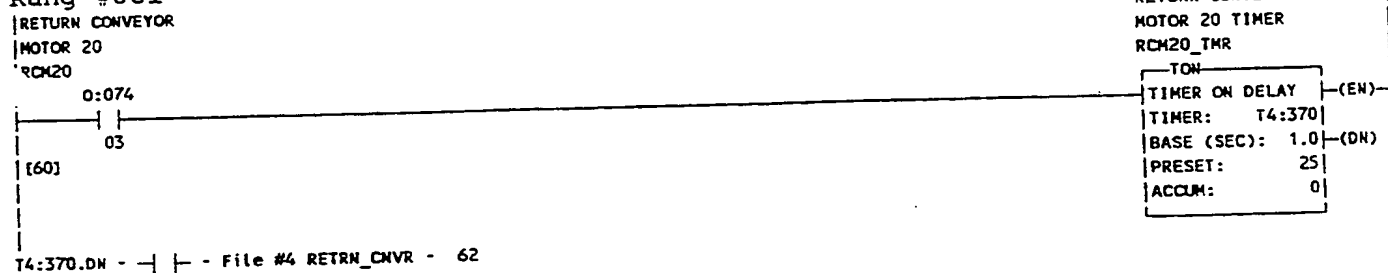
Rung #059



Rung #060



Rung #061



599

Rung #062

RCM20_TMR
T4:370

DN

RETURN CONVEYOR
MOTOR 20
RCM20

O:074

(U)
03

[61]

O:074/03 - | | - File #4 RETRN_CNVR - 61
 -(L)- File #4 RETRN_CNVR - 60
 -(U)- File #4 RETRN_CNVR - 62

Rung #063

AUTO RETURN RETURN CONVEYOR RETURN CONVEYOR
 CONVEYOR SENSOR 20 INDEXER READY
 AUTO_RC RCS20 IDX_RDY

83

1:066

1:066

RETURN CONVEYOR
INDEXER MOTOR
LATCH
RCIML

83

(L)
372

700

04

05

83/372 - | | - File #4 RETRN_CNVR - 65
 -|/| - File #4 RETRN_CNVR - 64
 -(L)- File #4 RETRN_CNVR - 63
 -(U)- File #4 RETRN_CNVR - 66

Rung #064

RETURN CONVEYOR
 INDEXER MOTOR
 LATCH
 RCIML

83

/|

372

RETURN CONVEYOR
INDEXER MOTOR
START
RCIMS

O:076

()
00

[63]

Rung #065

RETURN CONVEYOR
 INDEXER MOTOR
 LATCH
 RCIML

83

372

RETURN CONVEYOR
 INDEXER MOTOR
 TIMER
 RCIM_TMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:340
 BASE (SEC): 1.0 (DN)
 PRESET: 15
 ACCUM: 0

[66]

T4:340.DN - | | - File #4 RETRN_CNVR - 66

Rung #066

RCIM_TMR
 T4:340
 DN

RETURN CONVEYOR
 INDEXER MOTOR
 LATCH
 RCIML

83

(U)
372

[65]

83/372 - | | - File #4 RETRN_CNVR - 65
 -|/| - File #4 RETRN_CNVR - 64
 -(L)- File #4 RETRN_CNVR - 63
 -(U)- File #4 RETRN_CNVR - 66

Rung #067

RET
 RETURN ()

WO 92/17621

600

PCT/US92/00722

Rung #068

[END]-

601

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Rung #000

```

|AUTO
|MODE  MOTOR 3  PAUSE
|ENABLE FAST    DISABLE
|AUTO   M3F     TS12
|N7:37  0:012   N7:16
|-----|-----|/|
|11     12      4
|[2:158] [2:185] [2:3]
  
```

MOTOR 3
FAULT
TIMER
M3FLT

```

TON
TIMER ON DELAY (EN)
TIMER:  T4:303
BASE (SEC): 1.0 (DN)
PRESET:    100
ACCUM:     0
  
```

T4:303.DN - | | - File #5 FAULTS - 15

Rung #001

```

|AUTO
|MODE  MOTOR 4  PAUSE
|ENABLE FAST    DISABLE
|AUTO   M4F     TS12
|N7:37  0:012   N7:16
|-----|-----|/|
|11     13      4
|[2:158] [2:190] [2:3]
  
```

MOTOR 4
FAULT
TIMER
M4FLT

```

TON
TIMER ON DELAY (EN)
TIMER:  T4:304
BASE (SEC): 1.0 (DN)
PRESET:    100
ACCUM:     0
  
```

T4:304.DN - | | - File #5 FAULTS - 15

Rung #002

```

JTO
|MODE  MOTOR 5  PAUSE
|ENABLE FAST    DISABLE
|AUTO   M5F     TS12
|N7:37  0:012   N7:16
|-----|-----|/|
|11     14      4
|[2:158] [2:195] [2:3]
  
```

MOTOR 5
FAULT
TIMER
M5FLT

```

TON
TIMER ON DELAY (EN)
TIMER:  T4:305
BASE (SEC): 1.0 (DN)
PRESET:    100
ACCUM:     0
  
```

T4:305.DN - | | - File #5 FAULTS - 15

Rung #003

```

|AUTO
|MODE  MOTOR 6  PAUSE
|ENABLE FAST    DISABLE
|AUTO   M6F     TS12
|N7:37  0:012   N7:16
|-----|-----|/|
|11     15      4
|[2:158] [2:218] [2:3]
  
```

MOTOR 6 OR 7
FAULT
TIMER
M6,7FLT

```

TON
TIMER ON DELAY (EN)
TIMER:  T4:306
BASE (SEC): 1.0 (DN)
PRESET:    200
ACCUM:     62
  
```

```

MOTOR 7
FAST
M7F
0:012
16
[2:231]
  
```

T4:306.DN - | | - File #5 FAULTS - 15

602

Rung #004

AUTO
 MODE MOTOR 8 PAUSE
 ENABLE FAST DISABLE
 AUTO M8F TS12
 N7:37 0:012 N7:16

11 17 4
 [2:158] [2:249] [2:3]

MOTOR 8
 FAULT TIMER
 M8FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:335
 BASE (SEC): 1.0 (DN)
 PRESET: 200
 ACCUM: 4

T4:335.DN - | - File #5 FAULTS - 15

Rung #005

AUTO
 MODE MOTOR 9 PAUSE
 ENABLE FAST DISABLE
 AUTO M9F TS12
 N7:37 0:032 N7:16

11 10 4
 [2:158] [2:253] [2:3]

MOTOR 9
 FAULT FAULT
 M9FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:307
 BASE (SEC): 1.0 (DN)
 PRESET: 150
 ACCUM: 0

T4:307.DN - | - File #5 FAULTS - 15

Rung #006

0
 MODE MOTOR 10 PAUSE
 ENABLE FAST DISABLE
 AUTO M10F TS12
 N7:37 0:032 N7:16

11 11 4
 [2:158] [2:258] [2:3]

MOTOR 10 OR 11
 FAULT
 TIMER
 M10,11FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:308
 BASE (SEC): 1.0 (DN)
 PRESET: 200
 ACCUM: 0

MOTOR 11
 FAST
 M11F
 0:032
 12

[2:263]

T4:308.DN - | - File #5 FAULTS - 15

Rung #007

AUTO
 MODE MOTOR 12 PAUSE
 ENABLE FAST DISABLE
 AUTO M12F TS12
 N7:37 0:032 N7:16

11 13 4
 [2:158] [2:281] [2:3]

MOTOR 12
 FAULT TIMER
 M12FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:336
 BASE (SEC): 1.0 (DN)
 PRESET: 200
 ACCUM: 0

T4:336.DN - | - File #5 FAULTS - 15

603

Rung #008

AUTO
 MODE MOTOR 13 PAUSE
 ENABLE FAST DISABLE
 AUTO M13F TS12
 N7:37 0:032 N7:16
 11 14 4
 [2:158] [2:285] [2:3]

MOTOR 13
 FAULT TIMER
 M13FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:309
 BASE (SEC): 1.0 (DN)
 PRESET: 150
 ACCUM: 0

T4:309.DN - | - File #5 FAULTS - 15
 Rung #009

AUTO
 MODE MOTOR 14 PAUSE PALLET
 ENABLE FAST DISABLE RIGHT SIDE
 AUTO M14F TS12 CARBON
 N7:37 0:032 N7:16 I:053
 11 15 4 02
 [2:158] [2:290] [2:3]

MOTOR 14 OR 15
 FAULT TIMER
 M14,15FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:310
 BASE (SEC): 1.0 (DN)
 PRESET: 180
 ACCUM: 47

MOTOR 15
 FAST
 M15F
 0:032
 16
 [2:295]

T4:310.DN - | - File #5 FAULTS - 15
 Rung #010

AUTO
 MODE MOTOR 16 PAUSE PALLET
 ENABLE FAST DISABLE RIGHT SIDE
 AUTO M16F TS12 DWELL 6
 N7:37 0:032 N7:16 I:053
 11 17 4 05
 [2:158] [2:306] [2:3]

MOTOR 16
 FAULT TIMER
 M16FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:337
 BASE (SEC): 1.0 (DN)
 PRESET: 120
 ACCUM: 15

T4:337.DN - | - File #5 FAULTS - 15
 Rung #011

AUTO
 MODE MOTOR 17 PAUSE PALLET
 ENABLE FAST DISABLE RIGHT SIDE
 AUTO M17F TS12 BUFFER 4
 N7:37 0:062 N7:16 I:053
 11 10 4 10
 [2:158] [2:310] [2:3]

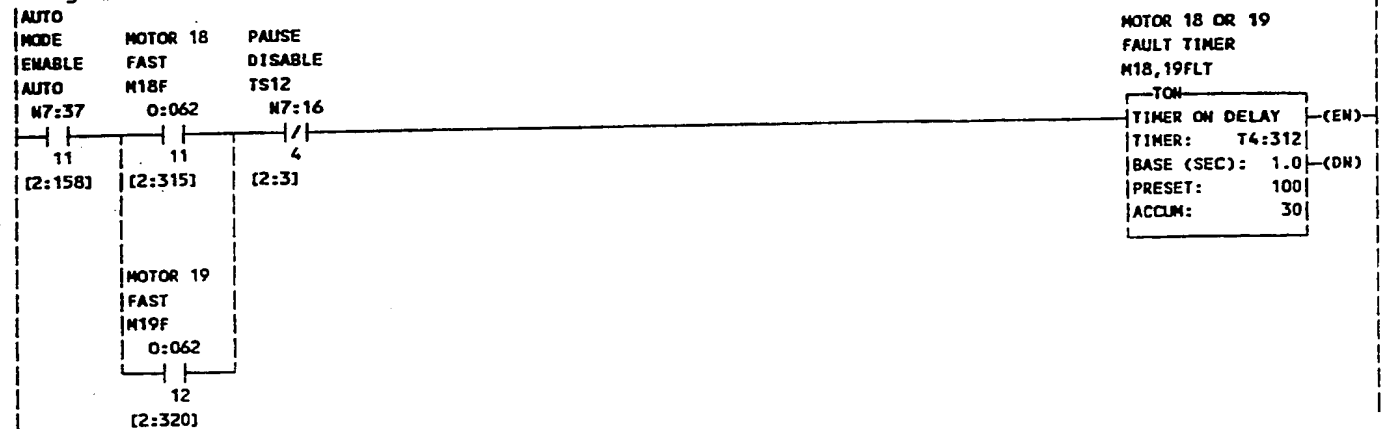
MOTOR 17
 FAULT TIMER
 M17FLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:311
 BASE (SEC): 1.0 (DN)
 PRESET: 130
 ACCUM: 0

T4:311.DN - | - File #5 FAULTS - 15

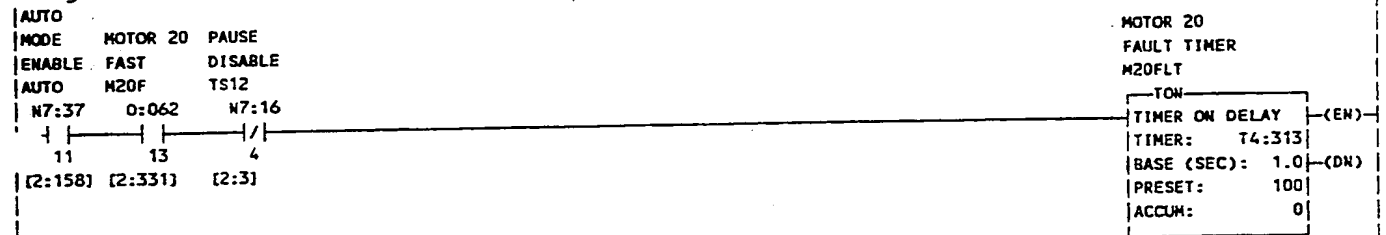
604

Rung #012



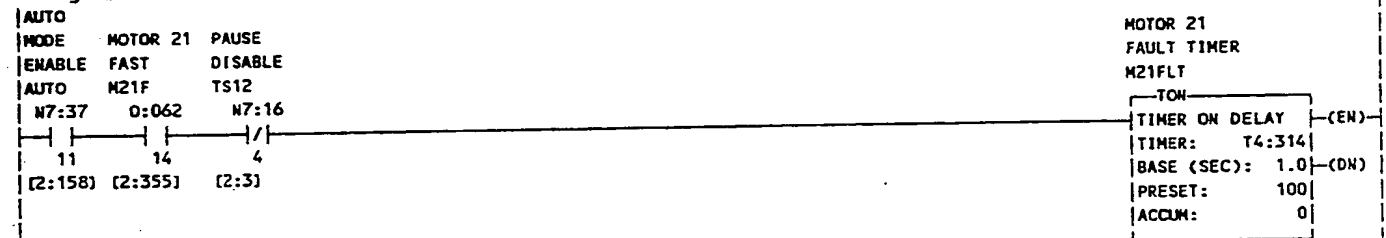
T4:312.DN - | - File #5 FAULTS - 15

Rung #013



T4:313.DN - | - File #5 FAULTS - 15

Rung #014



T4:314.DN - | - File #5 FAULTS - 15

605

Rung #015

MOTOR FAULT

TIMER DONE

MOTOR_FLT

83

(L)

811

M3FLT
T4:303

DN

[0]

B3/811 - | | - File #2 MAIN PRGRM - 626
-(U)- - File #5 FAULTS - 16M4FLT
T4:304

DN

[1]

M5FLT
T4:305

DN

[2]

M6,7FLT
T4:306

DN

[3]

M8FLT
T4:335

DN

[4]

M9FLT
T4:307

DN

[5]

M10,11FLT
T4:308

DN

[6]

M12FLT
T4:336

DN

[7]

M13FLT
T4:309

DN

[8]

M14,15FLT
T4:310

DN

[9]

M16FLT
T4:337

DN

[10]

606

Rung #016

PAUSE
DISABLE
TS12

N7:16

4
(2:3)

83/811 - | | - File #2 MAIN_PRGRM - 626

-(L)- File #5 FAULTS - 15

-(U)- File #5 FAULTS - 16

MOTOR FAULT

TIMER DONE

MOTOR_FLT

B3

(U)

811

Rung #017

DOOR CLOSE

SOLENOID

1 ENABLE

DRCL1

0:011

00

(2:183)

DOOR 1

CLOSE

TIMER

D1CLTMR

TON

TIMER ON DELAY

TIMER: T4:81

BASE (SEC): 1.0

PRESET: 4

ACCUM: 0

(EN)

(DN)

T4:81.DN - | | - File #5 FAULTS - 18

Rung #018

FAULT

DETECT

DR 1 DOOR 1

CLOSED CLOSED

D1CLTMR DRCL1S

T4:81 1:006

DN 00

(17)

83/201 - | | - File #5 FAULTS - 65

-() - File #5 FAULTS - 18

DOOR 1

CLOSED

FAULT

D1CLFLT

B3

()

201

Rung #019

DOOR CLOSE

SOLENOID

2 ENABLE

DRCL2

0:011

02

(2:202)

DOOR 2

CLOSE

TIMER

D2CLTMR

TON

TIMER ON DELAY

TIMER: T4:82

BASE (SEC): 1.0

PRESET: 4

ACCUM: 0

(EN)

(DN)

T4:82.DN - | | - File #5 FAULTS - 20

Rung #020

FAULT

DETECT

DOOR 2 DOOR 2

CLOSED CLOSED

D2CLTMR DRCL2S

T4:82 1:006

DN 02

(19)

83/202 - | | - File #5 FAULTS - 65

-() - File #5 FAULTS - 20

DOOR 2

CLOSED

FAULT

D2CLFLT

B3

()

202

607

Rung #021

CLOSE
DOOR 3
DRCL3
0:011

04
[2:229]

DOOR 3
CLOSE
TIMER
D3CLTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:83
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

T4:83.DN - | | - File #5 FAULTS - 22

Rung #022

FAULT
DETECT
DOOR 3 DOOR 3
CLOSED CLOSED
D3CLTMR DRCL3S
T4:83 1:006

DN 04

[21]

83/203 - | | - File #5 FAULTS - 65

- () - File #5 FAULTS - 22

Rung #023

DOOR CLOSE

ENOID
4 ENABLE
DRCL4
0:011

06
[2:408]

DOOR 4
CLOSE
TIMER
D4CLTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:84
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

T4:84.DN - | | - File #5 FAULTS - 24

Rung #024

FAULT
DETECT
DOOR 4 DOOR 4
CLOSED CLOSED
D4CLTMR DRCL4S
T4:84 1:006

DN 06

[23]

84/204 - | | - File #5 FAULTS - 65

- () - File #5 FAULTS - 24

Rung #025

DOOR CLOSE
SOLENOID
5 ENABLE
DRCL5
0:031

00
[2:414]

DOOR 5
CLOSE
TIMER
D5CLTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:85
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

608

T4:85.DN - - File #5 FAULTS - 26

Rung #026

FAULT
DETECT
DOOR 5 DOOR 5
CLOSED CLOSED
D5CLTMR DRCL5S
T4:85 1:026

DOOR 5
CLOSED
FAULT
D5CLFLT
83
()
205

DN 00

[25]

83/205 - - File #5 FAULTS - 65

- () - File #5 FAULTS - 26

Rung #027

DOOR CLOSE
SOLENOID
6 ENABLE
DRCL6

DOOR 6
CLOSE
TIMER
D6CLTMR

0:031
02
[2:420]

TON
TIMER ON DELAY (EN)
TIMER: T4:86
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCU: 0

T4:86.DN - - File #5 FAULTS - 28

Rung #028

JLT
DETECT
DOOR 6 DOOR 6
CLOSED CLOSED
D6CLTMR DRCL6S
T4:86 1:026

DOOR 6
CLOSED
FAULT
D6CLFLT
83
()
206

DN 02

[27]

83/206 - - File #5 FAULTS - 65

- () - File #5 FAULTS - 28

Rung #029

DOOR CLOSE
SOLENOID
7 ENABLE
DRCL7

DOOR 7
CLOSE
TIMER
D7CLTMR

0:045
00
[2:422]

TON
TIMER ON DELAY (EN)
TIMER: T4:87
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCU: 0

T4:87.DN - - File #5 FAULTS - 30

Rung #030

FAULT
DETECT
DOOR 7 DOOR 7
CLOSED CLOSED
D7CLTMR DRCL7S
T4:87 1:042

DOOR 7
CLOSED
FAULT
D7CLFLT
83
()
207

DN 00

[29]

83/207 - - File #5 FAULTS - 65

610

T4:90.DN - | | - File #5 FAULTS - 36
Rung #036

| FAULT
| DETECT
| DOOR 10 DOOR 10
| CLOSED CLOSED
| D10CLTMR DRCL10S
| T4:90 1:056
| | | / |
| DN 02

DOOR 10
CLOSED
FAULT
D10CLFLT
83
()
210

[35]
B3/210 - | | - File #5 FAULTS - 65
- () - File #5 FAULTS - 36
Rung #037

| CLOSE
| DOOR 11
| DRCL11
| 0:061
| | |
| 04
| [2:337]

DOOR 11
CLOSE
TIMER
D11CLTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:91
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

21.DN - | | - File #5 FAULTS - 38
Rung #038

| FAULT
| DETECT
| DOOR 11 DOOR 11
| CLOSED CLOSED
| D11CLTMR DRCL11S
| T4:91 1:056
| | | / |
| DN 04

DOOR 11
CLOSED
FAULT
D11CLFLT
83
()
211

[37]
B3/211 - | | - File #5 FAULTS - 65
- () - File #5 FAULTS - 38
Rung #039

| DOOR CLOSE
| SOLENOID12
| ENABLE
| DRCL12
| 0:061
| | |
| 06
| [2:353]

DOOR 12
CLOSE
TIMER
D12CLTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:92
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

T4:92.DN - | | - File #5 FAULTS - 40
Rung #040

| FAULT
| DETECT DOOR 12
| DOOR 12 CLOSED
| D12CLTMR DRCL12S
| T4:92 1:056
| | | / |
| DN 06

DOOR 12
CLOSED
FAULT
D12CLFLT
83
()
212

[39]

611

83/212 - | | - File #5 FAULTS - 65
 - () - File #5 FAULTS - 40

Rung #041

OPEN DOOR

1

DROP1

O:011

01

[2:181]

DOOR 1
 OPEN
 TIMER
 D1OPTMR

TON	(EN)
TIMER ON DELAY	
TIMER: T4:101	
BASE (SEC): 1.0	(DN)
PRESET: 4	
ACCUM: 0	

T4:101.DN - | | - File #5 FAULTS - 42

Rung #042

FAULT

DETECTED

DOOR 1 DOOR 1

OPEN OPEN

D1OPTMR DROP1S

T4:101 I:006

DN

01

[41]

DOOR 1
 OPEN
 FAULT
 D1OPFLT
 83
 ()
 221

83/221 - | | - File #5 FAULTS - 66
 - () - File #5 FAULTS - 42

Rung #043

OPEN DOOR

SOLENOID

2 ENABLE

DROP2

O:011

03

[2:200]

DOOR 2
 OPEN
 TIMER
 D2OPTMR

TON	(EN)
TIMER ON DELAY	
TIMER: T4:102	
BASE (SEC): 1.0	(DN)
PRESET: 4	
ACCUM: 2	

T4:102.DN - | | - File #5 FAULTS - 44

Rung #044

FAULT

DETECT

DOOR 2 DOOR 2

OPEN OPEN

D2OPTMR DROP2S

T4:102 I:006

DN

03

[3]

DOOR 2
 OPEN
 FAULT
 D2OPFLT
 83
 ()
 222

83/222 - | | - File #5 FAULTS - 66
 - () - File #5 FAULTS - 44

Rung #045

DOOR OPEN

SOLENOID

3 ENABLE

DROP3

O:011

05

[2:216]

DOOR 3
 OPEN
 TIMER
 D3OPTMR

TON	(EN)
TIMER ON DELAY	
TIMER: T4:103	
BASE (SEC): 1.0	(DN)
PRESET: 4	
ACCUM: 0	

612

T4:103.DN - - File #5 FAULTS - 46

Rung #046

FAULT
 DETECT
 DOOR 3 DOOR 3
 OPEN OPEN
 D3OPTMR DROP3S
 T4:103 1:006
 DN 05

DOOR 3
 OPEN
 FAULT
 D3OPFLT
 B3
 223

[45]

B3/223 - - File #5 FAULTS - 66

- () - - File #5 FAULTS - 46

Rung #047

DOOR OPEN
 SOLENOID
 4 ENABLE
 DROP4
 0:011
 07

DOOR 4
 OPEN
 TIMER
 D4OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:104
 BASE (SEC): 1.0 (DN)
 PRESET: 4
 ACCUM: 0

[2:415]

T4.DN - - File #5 FAULTS - 48

Rung #048

FAULT
 DETECT
 DOOR 4 DOOR 4
 OPEN OPEN
 D4OPTMR DROP4S
 T4:104 1:006
 DN 07

DOOR 4
 OPEN
 FAULT
 D4OPFLT
 B3
 224

[47]

B3/224 - - File #5 FAULTS - 66

- () - - File #5 FAULTS - 48

Rung #049

DOOR OPEN
 SOLENOID
 5 ENABLE
 DROPS
 0:031
 01

DOOR 5
 OPEN
 TIMER
 D5OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:105
 BASE (SEC): 1.0 (DN)
 PRESET: 4
 ACCUM: 0

[2:46]

T4:105.DN - - File #5 FAULTS - 50

Rung #050

FAULT
 DETECT
 DOOR 5 DOOR 5
 OPEN OPEN
 D5OPTMR DROP5S
 T4:105 1:026
 DN 01

DOOR 5
 OPEN
 FAULT
 D5OPFLT
 B3
 225

[49]

613

83/225 - 4/1 - File #5 FAULTS - 66
 - () - File #5 FAULTS - 50

Rung #051

```
DOOR OPEN
SOLENOID
6 ENABLE
DROP6
```

0:031

03

12:47

DOOR 6
OPEN
TIMER
D6OPTMR

```

TON
-----
TIMER ON DELAY (EN)
TIMER:      T4:106
BASE (SEC): 1.0 (DN)
PRESET:      4
ACCUM:       0

```

T4:106.DN - 1 - File #5 FAULTS - 52
Rung #052

FAULT	
DETECT	
DOOR 6	DOOR 6
OPEN	OPEN
D6OPTMR	DROP6S
T4:106	1:026

DN 03

[51]

DOOR 6
OPEN
FAULT
D6OPFLT
B3

226

83/226 - 1/1 - File #5 FAULTS - 66
 - () - File #5 FAULTS - 52

.ng #053

```
|DOOR OPEN
|SOLENOID
|7 ENABLE
|DROP7
```

0:045

01

[2:48]

DOOR 7
OPEN
TIMER
D7OPTMR

TON		
TIMER ON DELAY		(EN)
TIMER: T4:107		
BASE (SEC): 1.0		(DN)
PRESET: 4		
ACCU: 0		

T4:107.DN - 1 - File #5 FAULTS - 54
Rung #054

FAULT	
DETECT	
DOOR 7	DOOR 7
OPEN	OPEN
D7OPTMR	DROP7S
T4:107	1:042

DN	01
----	----

.531

DOOR 7
OPEN
FAULT
D7OPFLT
53

227

83/227 - 1/1 - File #5 FAULTS - 66
 - () - File #5 FAULTS - 54

Rung #055

```
|DOOR OPEN
|SOLENOID
|8 ENABLE
|DROPS
```

0:045

03

12:49

DOOR 8
OPEN
TIMER
D8OPTMR

TON		
TIMER ON DELAY		(EN)
TIMER:	T4:108	
BASE (SEC):	1.0	(DN)
PRESET:	4	
ACCUM:	0	

>>>>>>>>>>>>>>>>>>>

614

T4:108.DN - | | - File #5 FAULTS - 56

Rung #056

FAULT
DETECT
DOOR 8 DOOR 8
OPEN OPEN
D8OPTMR DROPS
T4:108 1:042
DN 03

DOOR 8
OPEN
FAULT
D8OPFLT
83
()
228

[55]

83/228 - | | - File #5 FAULTS - 66

-() - File #5 FAULTS - 56

Rung #057

DOOR OPEN
SOLENOID
9 ENABLE
DROP9
0:061
01
[2:325]

DOOR 9
OPEN
TIMER
D9OPTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:109
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

109.DN - | | - File #5 FAULTS - 58

Rung #058

FAULT
DETECT
DOOR 9 DOOR 9
OPEN OPEN
D9OPTMR DROPS
T4:109 1:056
DN 01

DOOR 9
OPEN
FAULT
D9OPFLT
83
()
229

[57]

83/229 - | | - File #5 FAULTS - 66

-() - File #5 FAULTS - 58

Rung #059

DOOR OPEN
SOLENOID
10 ENABLE
DROP10
0:061
03
[2:326]

DOOR 10
OPEN
TIMER
D10OPTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:110
BASE (SEC): 1.0 (DN)
PRESET: 4
ACCUM: 0

T4:110.DN - | | - File #5 FAULTS - 60

Rung #060

FAULT
DETECT
DOOR 10 DOOR 10
OPEN OPEN
D10OPTMR DROP10S
T4:110 1:056
DN 03

DOOR 10
OPEN
FAULT
D10OPFLT
83
()
230

[59]

615

B3/230 - \neg / \neg - File #5 FAULTS - 66
 () - File #5 FAULTS - 60

Rung #061

DOOR OPEN
 SOLENOID
 11 ENABLE
 DROP11

O:061

05

[2:327]

DOOR 11
 OPEN
 TIMER
 D11OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:111
 BASE (SEC): 1.0 (DN)
 PRESET: 4
 ACCUM: 0

T4:111.DN - \neg / \neg - File #5 FAULTS - 62

Rung #062

FAULT
 DETECT
 DOOR 11 DOOR 11
 OPEN OPEN
 D11OPTMR DROP11S
 T4:111 I:056

DN

05

[61]

DOOR 11
 OPEN
 FAULT
 D11OPFLT
 83
 ()
 231

B3/231 - \neg / \neg - File #5 FAULTS - 66
 () - File #5 FAULTS - 62

ng #063

DOOR OPEN
 SOLENOID
 12 ENABLE
 DROP12

O:061

07

[2:351]

DOOR 12
 OPEN
 TIMER
 D12OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:112
 BASE (SEC): 1.0 (DN)
 PRESET: 4
 ACCUM: 0

T4:112.DN - \neg / \neg - File #5 FAULTS - 64

Rung #064

FAULT
 DETECT
 DOOR 12 DOOR 12
 OPEN OPEN
 D12OPTMR DROP12S
 T4:112 I:056

DN

07

[53]

DOOR 12
 OPEN
 FAULT
 D12OPFLT
 83
 ()
 232

B3/232 - \neg / \neg - File #5 FAULTS - 66
 () - File #5 FAULTS - 64

Rung #065

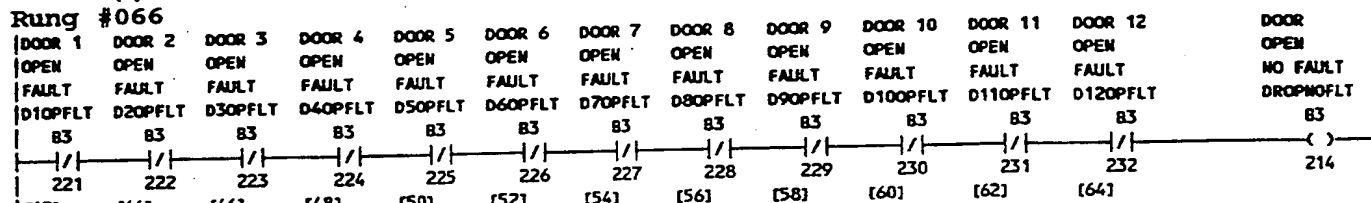
DOOR 1	DOOR 2	DOOR 3	DOOR 4	DOOR 5	DOOR 6	DOOR 7	DOOR 8	DOOR 9	DOOR 10	DOOR 11	DOOR 12	DOOR
CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED
FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	NO FAULT
D1CLFLT	D2CLFLT	D3CLFLT	D4CLFLT	D5CLFLT	D6CLFLT	D7CLFLT	D8CLFLT	D9CLFLT	D10CLFLT	D11CLFLT	D12CLFLT	DRCLNOFLT
83	83	83	83	83	83	83	83	83	83	83	83	83
/	/	/	/	/	/	/	/	/	/	/	/	()
201	202	203	204	205	206	207	208	209	210	211	212	213
[18]	[20]	[22]	[24]	[26]	[28]	[30]	[32]	[34]	[36]	[38]	[40]	

B3/213 - \neg / \neg - File #5 FAULTS - 67

616

-() - File #5 FAULTS - 65

Rung #066



83/214 - |/| - File #5 FAULTS - 67

-() - File #5 FAULTS - 66

Rung #067



[65]

83/215 - | | - File #2 MAIN_PRGRM - 625
 |/| - File #2 MAIN_PRGRM - 158
 -(U) - File #5 FAULTS - 68

DOOR
 OPEN
 NO FAULT
 DROPNOFLT

83
 |/|
 214

[66]

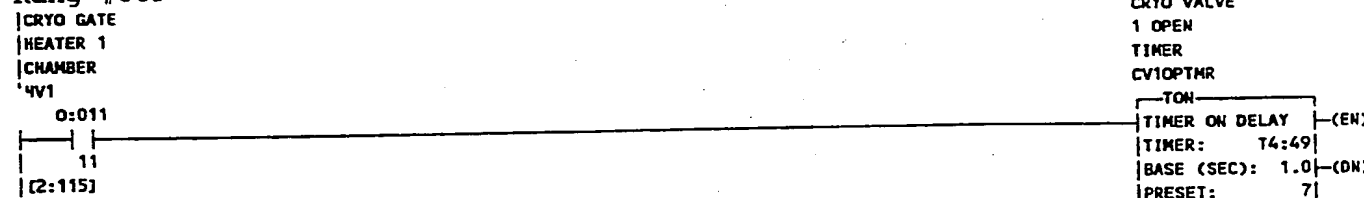
Rung #068



[2:3]

83/215 - | | - File #2 MAIN_PRGRM - 625
 |/| - File #2 MAIN_PRGRM - 158
 -(L) - File #5 FAULTS - 67
 -(U) - File #5 FAULTS - 68

Rung #069



T4:49.DN - | | - File #5 FAULTS - 70

617

Rung #070

FAULT HEATER 1
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 1 OPEN OPEN
 CV1OPTMR HV1S3

CRYO VALVE
 1 OPEN
 FAULT
 CV1OPFLT

T4:49 1:002

DN 10

83
 251

[69]

B3/251 - | | - File #5 FAULTS - 93

-() - File #5 FAULTS - 70

Rung #071

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 HEATER 2 HEATER 2
 CHAMBER CHAMBER
 HV2_1 HV2_2

CRYO VALVE
 2 OPEN
 TIMER
 CV2OPTMR

0:011 0:011

13 14

[2:117] [2:118]

TON
 TIMER ON DELAY (EN)
 TIMER: T4:50
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:50.DN - | | - File #5 FAULTS - 72

Rung #072

ILT HEATER 2
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 2 OPEN OPEN
 CV2OPTMR HV2S3

CRYO VALVE
 2 OPEN
 FAULT
 CV2OPFLT

T4:50 1:004

DN 02

83
 252

[71]

B3/252 - | | - File #5 FAULTS - 93

-() - File #5 FAULTS - 72

Rung #073

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 1 DWELL 1
 CHAMBER CHAMBER
 HV3_1 HV3_2

CRYO VALVE
 3 OPEN
 TIMER
 CV3OPTMR

0:011 0:011

15 16

[2:119] [2:120]

TON
 TIMER ON DELAY (EN)
 TIMER: T4:51
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:51.DN - | | - File #5 FAULTS - 74

Rung #074

FAULT DWELL 1
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 3 OPEN OPEN
 CV3OPTMR HV3S3

CRYO VALVE
 3 OPEN
 FAULT
 CV3OPFLT

T4:51 1:004

DN 05

83
 253

[73]

618

83/253 - -|/| - File #5 FAULTS - 93
-() - File #5 FAULTS - 74

Rung #075

CRYO GATE CRYO GATE
SOLENOID 1 SOLENOID 2
DWELL 2 DWELL 2
CHAMBER CHAMBER
HV4_1 HV4_2

0:031 0:031

11 12
[2:121] [2:122]

CRYO VALVE
4 OPEN
TIMER
CV4OPTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:52
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCU: 0

T4:52.DN - -|/| - File #5 FAULTS - 76

Rung #076

FAULT DWELL 2
DETECT CHAMBER
CRYO VALVE GATE VALVE
4 OPEN OPEN
CV4OPTMR HV4S3

T4:52 1:022

DN 10

[75]

CRYO VALVE
4 OPEN
FAULT
CV4OPFLT
83

()

254

83/254 - -|/| - File #5 FAULTS - 93
-() - File #5 FAULTS - 76

Rung #077

CRYO GATE CRYO GATE
SOLENOID 1 SOLENOID 2
HEATER 2 HEATER 2
CHAMBER CHAMBER
HVS_1 HVS_2

0:031 0:031

13 14
[2:123] [2:124]

CRYO VALVE
5 OPEN
TIMER
CV5OPTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:53
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCU: 0

T4:53.DN - -|/| - File #5 FAULTS - 78

Rung #078

FAULT HEATER 3
DETECT CHAMBER
CRYO VALVE GATE VALVE
5 OPEN OPEN
CV5OPTMR HV5S3

T4:53 1:024

DN 02

[77]

CRYO VALVE
5 OPEN
FAULT
CV5OPFLT
83

()

255

83/255 - -|/| - File #5 FAULTS - 93
-() - File #5 FAULTS - 78

619

Rung #079

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 3 DWELL 3
 CHAMBER CHAMBER
 HV6_1 HV6_2

0:031 0:031
 15 16
 (2:125) (2:126)

CRYO VALVE
 6 OPEN
 TIMER
 CV6OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:54
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:54.DN - | | - File #5 FAULTS - 80

Rung #080

FAULT DWELL 3
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 6 OPEN OPEN
 CV6OPTMR HV6S3

T4:54 1:024
 DN 05

CRYO VALVE
 6 OPEN
 FAULT
 CV6OPFLT
 83

()

256

[79]

B3/256 - | | - File #5 FAULTS - 93

- () - File #5 FAULTS - 80

Rung #081

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 4 DWELL 4
 CHAMBER CHAMBER
 HV7_1 HV7_2

0:045 0:045
 11 12
 (2:127) (2:128)

CRYO VALVE
 7 OPEN
 TIMER
 CV7OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:55
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:55.DN - | | - File #5 FAULTS - 82

Rung #082

FAULT DWELL 4
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 7 OPEN OPEN
 CV7OPTMR HV7S3

T4:55 1:036
 DN 10

CRYO VALVE
 7 OPEN
 FAULT
 CV7OPFLT
 83

()

257

[81]

B3/257 - | | - File #5 FAULTS - 93

- () - File #5 FAULTS - 82

620

Rung #083

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 BUFFER 3 BUFFER 3
 CHAMBER CHAMBER
 HV8_1 HV8_2

0:045 0:045
 13 14
 [2:129] [2:130]

CRYO VALVE
 8 OPEN
 TIMER
 CV8OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:56
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:56.DN - | | - File #5 FAULTS - 84

Rung #084

FAULT BUFFER 3
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 8 OPEN OPEN
 CV8OPTMR HV8S3

T4:56 1:040
 DN 02

CRYO VALVE
 8 OPEN
 FAULT
 CV8OPFLT
 83
 258

[83]

83/258 - | | - File #5 FAULTS - 93

- () - File #5 FAULTS - 84

Rung #085

YO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 5 DWELL 5
 CHAMBER CHAMBER
 HV9_1 HV9_2

0:045 0:045
 15 16
 [2:131] [2:132]

CRYO VALVE
 9 OPEN
 TIMER
 CV9OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:57
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:57.DN - | | - File #5 FAULTS - 86

Rung #086

FAULT DWELL 5
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 9 OPEN OPEN
 CV9OPTMR HV9S3

T4:57 1:040
 DN 05

CRYO VALVE
 9 OPEN
 FAULT
 CV9OPFLT
 83
 259

[85]

83/259 - | | - File #5 FAULTS - 93

- () - File #5 FAULTS - 86

621

Rung #087

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 6 DWELL 6
 CHAMBER CHAMBER
 HV10_1 HV10_2
 0:061 0:061

11 12
 [2:133] [2:134]

CRYO VALVE
 10 OPEN
 TIMER
 CV10OPTRM

TON
 TIMER ON DELAY (EN)
 TIMER: T4:58
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:58.DN - | | - File #5 FAULTS - 88

Rung #088

FAULT DWELL 6
 DETEC CHAMBER
 CRYO VALVE GATE VALVE
 10 OPEN OPEN
 CV10OPTRM HV10S3
 T4:58 1:052

DN 10

CRYO VALVE
 10 OPEN
 FAULT
 CV10OPFLT
 83

260

[87]

83/260 - | | - File #5 FAULTS - 93

-() - File #5 FAULTS - 88

Rung #089

YO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 BUFFER 4 BUFFER 4
 CHAMBER CHAMBER
 HV11_1 HV11_2
 0:061 0:061

13 14
 [2:135] [2:136]

CRYO VALVE
 11 OPEN
 TIMER
 CV11OPTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:59
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:59.DN - | | - File #5 FAULTS - 90

Rung #090

FAULT BUFFER 4
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 11 OPEN OPEN
 CV11OPTMR HV11S3
 T4:59 1:054

DN 02

CRYO VALVE
 11 OPEN
 FAULT
 CV11OPFLT
 83

261

[89]

83/261 - | | - File #5 FAULTS - 93

-() - File #5 FAULTS - 90

622

Rung #091

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 EXBUFFER EXBUFFER
 CHAMBER CHAMBER
 HV12_1 HV12_2
 0:061 0:061

15 16
 [2:137] [2:138]

CRYO VALVE
 12 OPEN
 TIMER
 CV120PTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:60
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:60.DN - | | - File #5 FAULTS - 92

Rung #092

FAULT EXIT
 DETECT BUFFER
 CRYO VALVE GATE VALVE
 12 OPEN OPEN
 CV120PTMR HV12S3
 T4:60 1:054

DN 05

CRYO VALVE
 12 OPEN
 FAULT
 CV120PFLT
 83
 262

[91]

83/262 - | | - File #5 FAULTS - 93

- () - File #5 FAULTS - 92

Rung #093

CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE
OPEN	2 OPEN	3 OPEN	4 OPEN	5 OPEN	6 OPEN	7 OPEN	8 OPEN	9 OPEN	10 OPEN	
FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	
CV10PFLT	CV20PFLT	CV30PFLT	CV40PFLT	CV50PFLT	CV60PFLT	CV70PFLT	CV80PFLT	CV90PFLT	CV100PFLT	
83	83	83	83	83	83	83	83	83	83	
251	252	253	254	255	256	257	258	259	260	

[70]

[72]

[74]

[76]

[78]

[80]

[82]

[84]

[86]

[88]

CRYO VALVE CRYO VALVE
 11 OPEN 12 OPEN CRYO VALVE
 FAULT FAULT OPEN FAULT
 CV110PFLT CV120PFLT CVOPFLT
 83 83 83
 261 262 312
 [90] [92]

83/312 - | | - File #5 FAULTS - 142

- () - File #5 FAULTS - 93

Rung #094

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 HEATER 2 HEATER 2
 CHAMBER CHAMBER
 HV2_1 HV2_2
 0:011 0:011

13 14
 [2:117] [2:118]

CRYO VALVE
 2 THROTTLE
 TIMER
 CV2THTHR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:114
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 5

T4:114.DN - | | - File #5 FAULTS - 95

623

Rung #095

FAULT HEATER 2
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 2 THROTTLE THROTTLED
 CV2THTMR HV2S2

CRYO VALVE
 2 THROTTLE
 FAULT
 CV2THFLT
 83

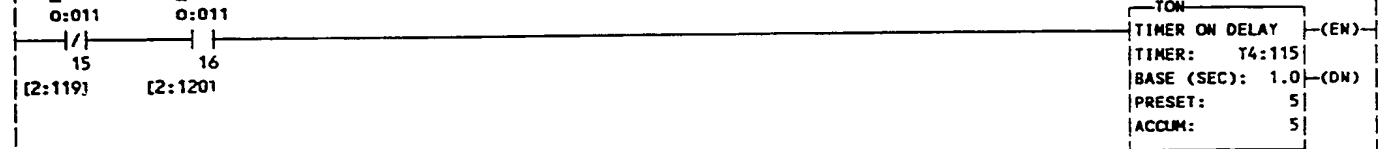


B3/234 - | | - File #5 FAULTS - 116
 - () - File #5 FAULTS - 95

Rung #096

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 1 DWELL 1
 CHAMBER CHAMBER
 HV3_1 HV3_2

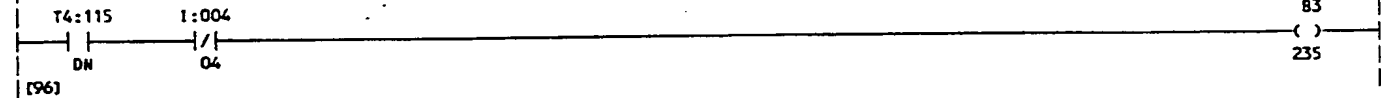
CRYO VALVE
 3 THROTTLE
 TIMER
 CV3THTMR



T4:115.DN - | | - File #5 FAULTS - 97
 Rung #097

ULT DWELL 1
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 3 THROTTLE THROTTLED
 CV3THTMR HV3S2

CRYO VALVE
 3 THROTTLE
 FAULT
 CV3THFLT
 83

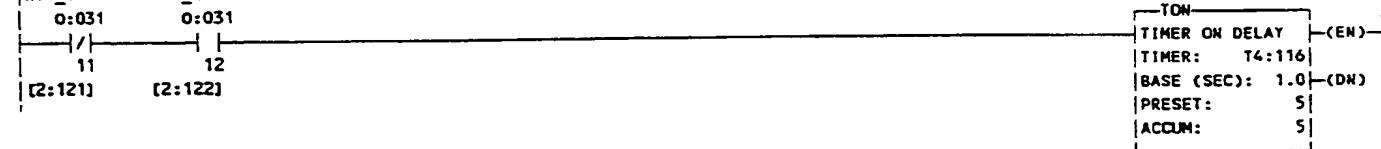


B3/235 - | | - File #5 FAULTS - 116
 - () - File #5 FAULTS - 97

Rung #098

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 2 DWELL 2
 CHAMBER CHAMBER
 HV4_1 HV4_2

CRYO VALVE
 4 THROTTLE
 TIMER
 CV4THTMR



T4:116.DN - | | - File #5 FAULTS - 99
 Rung #099

FAULT DWELL 2
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 4 THROTTLE THROTTLED
 CV4THTMR HV4S2

CRYO VALVE
 4 THROTTLE
 FAULT
 CV4THFLT
 83



[98]

624

B3/236 - -|/| - File #5 FAULTS - 116
 - () - File #5 FAULTS - 99

Rung #100

|CRYO GATE CRYO GATE
 |SOLENOID 1 SOLENOID 2
 |HEATER 2 HEATER 2
 |CHAMBER CHAMBER
 |HVS_1 HVS_2
 | 0:031 0:031
 | 13 14
 |[2:123] [2:124]

CRYO VALVE
 5 THROTTLE
 TIMER
 CV5THMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:117
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 5

T4:117.DN - -|/| - File #5 FAULTS - 101
 Rung #101

|FAULT HEATER 3
 |DETECT CHAMBER
 |CRYO VALVE GATE VALVE
 |5 THROTTLE THROTTLED
 |CV5THMR HV5S2
 | T4:117 I:024
 | DN 01

CRYO VALVE
 5 THROTTLE
 FAULT
 CV5THFLT
 83

237

B3/237 - -|/| - File #5 FAULTS - 116
 - () - File #5 FAULTS - 101

Rung #102

|CRYO GATE CRYO GATE
 |SOLENOID 1 SOLENOID 2
 |DWELL 3 DWELL 3
 |CHAMBER CHAMBER
 |HV6_1 HV6_2
 | 0:031 0:031
 | 15 16
 |[2:125] [2:126]

CRYO VALVE
 6 THROTTLE
 TIMER
 CV6THMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:118
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 5

T4:118.DN - -|/| - File #5 FAULTS - 103
 Rung #103

|FAULT DWELL 3
 |DETECT CHAMBER
 |CRYO VALVE GATE VALVE
 |6 THROTTLE THROTTLED
 |CV6THMR HV6S2
 | T4:118 I:024
 | DN 04

CRYO VALVE
 6 THROTTLE
 FAULT
 CV6THFLT
 83

238

B3/238 - -|/| - File #5 FAULTS - 116
 - () - File #5 FAULTS - 103

625

Rung #104

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 4 DWELL 4
 CHAMBER CHAMBER
 HV7_1 HV7_2

0:045 0:045
 11 12
 (2:127) (2:128)

CRYO VALVE
 7 THROTTLE
 TIMER
 CV7THTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:119
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 5

T4:119.DN - | | - File #5 FAULTS - 105

Rung #105

FAULT DWELL 4
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 7 THROTTLE THROTTLED
 CV7THTMR HV7S2

T4:119 1:036
 DN 07

CRYO VALVE
 7 THROTTLE
 FAULT
 CV7THFLT
 83

() 239

[104]

83/239 - | | - File #5 FAULTS - 116
 () - File #5 FAULTS - 105

Rung #106

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 BUFFER 3 BUFFER 3
 CHAMBER CHAMBER
 HV8_1 HV8_2

0:045 0:045
 13 14
 (2:129) (2:130)

CRYO VALVE
 8 THROTTLE
 TIMER
 CV8THTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:120
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 5

T4:120.DN - | | - File #5 FAULTS - 107

Rung #107

FAULT BUFFER 3
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 8 THROTTLE THROTTLED
 CV8THTMR HV8S2

T4:120 1:040
 DN 01

CRYO VALVE
 8 THROTTLE
 FAULT
 CV8THFLT
 83

() 240

[106]

83/240 - | | - File #5 FAULTS - 116
 () - File #5 FAULTS - 107

626

Rung #108

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 5 DWELL 5
 CHAMBER CHAMBER
 HV9_1 HV9_2

0:045 0:045
 15 16
 [2:131] [2:132]

CRYO VALVE
 9 THROTTLE
 TIMER
 CV9THTHR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:121
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 5

T4:121.DN - | | - File #5 FAULTS - 109

Rung #109

FAULT DWELL 5
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 9 THROTTLE THROTTLED
 CV9THTHR HV9S2

T4:121 1:040
 DN 04
 [108]

CRYO VALVE
 9 THROTTLE
 FAULT
 CV9THFLT
 83
 241

83/241 - | | - File #5 FAULTS - 116

-() - File #5 FAULTS - 109

Rung #110

O GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 6 DWELL 6
 CHAMBER CHAMBER
 HV10_1 HV10_2

0:061 0:061
 11 12
 [2:133] [2:134]

CRYO VALVE
 10THROTTLE
 TIMER
 CV10THTHR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:122
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:122.DN - | | - File #5 FAULTS - 111

Rung #111

FAULT DWELL 6
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 10THROTTLE THROTTLED
 CV10THTHR HV10S2

T4:122 1:052
 DN 07

CRYO VALVE
 10THROTTLE
 FAULT
 CV10THFLT
 83
 242

83/242 - | | - File #5 FAULTS - 116

-() - File #5 FAULTS - 111

627

Rung #112

CRYO GATE CRYO GATE
SOLENOID 1 SOLENOID 2
BUFFER 4 BUFFER 4
CHAMBER CHAMBER
HV11_1 HV11_2

0:061 0:061
13 14
[2:135] [2:136]

CRYO VALVE
11THROTTLE
TIMER
CV11THMTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:123
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 5

T4:123.DN - | | - File #5 FAULTS - 113

Rung #113

FAULT BUFFER 4
DETECT CHAMBER
CRYO VALVE GATE VALVE
11THROTTLE THROTTLED
CV11THMTMR HV11S2

T4:123 1:054
DN 01

CRYO VALVE
11THROTTLE
FAULT
CV11THFLT

83
()
243

[112]

B3/243 - | | - File #5 FAULTS - 116

-() - File #5 FAULTS - 113

Rung #114

CRYO GATE CRYO GATE
SOLENOID 1 SOLENOID 2
EXBUFFER EXBUFFER
CHAMBER CHAMBER
HV12_1 HV12_2

0:061 0:061
15 16
[2:137] [2:138]

CRYO VALVE
12THROTTLE
TIMER
CV12THMTMR

TON
TIMER ON DELAY (EN)
TIMER: T4:124
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 5

T4:124.DN - | | - File #5 FAULTS - 115

Rung #115

FAULT EXIT
DETECT BUFFER
CRYO VALVE GATE VALVE
12THROTTLE THROTTLED
CV12THMTMR HV12S2

T4:124 1:054
DN 04

CRYO VALVE
12THROTTLE
FAULT
CV12THFLT

83
()
244

[14]

B3/244 - | | - File #5 FAULTS - 116

-() - File #5 FAULTS - 115

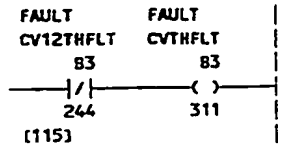
Rung #116

CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE CRYO VALVE
2 THROTTLE 3 THROTTLE 4 THROTTLE 5 THROTTLE 6 THROTTLE 7 THROTTLE 8 THROTTLE 9 THROTTLE 10THROTTLE 11THROTTLE
FAULT FAULT FAULT FAULT FAULT FAULT FAULT FAULT FAULT FAULT
CV2THFLT CV3THFLT CV4THFLT CV5THFLT CV6THFLT CV7THFLT CV8THFLT CV9THFLT CV10THFLT CV11THFLT

83 83 83 83 83 83 83 83 83 83
234 235 236 237 238 239 240 241 242 243
[95] [97] [99] [101] [103] [105] [107] [109] [111] [113]

CRYO VALVE CRYO VALVE
12THROTTLE THROTTLE

628



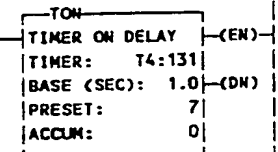
B3/311 - - File #5 FAULTS - 142
 - - File #5 FAULTS - 116

Rung #117

CRYO GATE
 HEATER 1
 CHAMBER
 HV1

O:011
 11
 [2:115]

CRYO VALVE
 1 CLOSE
 TIMER
 CV1CLTMR



T4:131.DN - - File #5 FAULTS - 118
 Rung #118

FAULT HEATER 1
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 1 CLOSE CLOSE
 1CLTMR HV1S1

T4:131 1:002
 DN 06
 [117]

CRYO VALVE
 1 CLOSE
 FAULT
 CV1CLFLT
 83

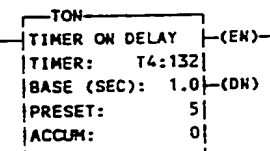
B3/151 - - File #5 FAULTS - 141
 - - File #5 FAULTS - 118

Rung #119

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 HEATER 2 HEATER 2
 CHAMBER CHAMBER
 HV2_1 HV2_2

O:011 O:011
 13 14
 [2:117] [2:118]

CRYO VALVE
 2 CLOSE
 TIMER
 CV2CLTMR



T4:132.DN - - File #5 FAULTS - 120
 Rung #120

AULT HEATER 2
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 2 CLOSE CLOSE
 CV2CLTMR HV2S1

T4:132 1:004
 DN 00
 [119]

CRYO VALVE
 2 CLOSE
 FAULT
 CV2CLFLT
 83

B3/152 - - File #5 FAULTS - 141
 - - File #5 FAULTS - 120

629

Rung #121

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 1 DWELL 1
 CHAMBER CHAMBER
 HV3_1 HV3_2

0:011 0:011
 15 16
 [2:119] [2:120]

CRYO VALVE
 3 CLOSE
 TIMER
 CV3CLTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:133
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:133.DN - | | - File #5 FAULTS - 122

Rung #122

FAULT DWELL 1
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 3 CLOSE CLOSED
 CV3CLTMR HV3S1

T4:133 1:004
 DN 03

CRYO VALVE
 3 CLOSED
 FAULT
 CV3CLFLT
 83
 153

[121]

83/153 - | | - File #5 FAULTS - 141

- () - File #5 FAULTS - 122

Rung #123

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 2 DWELL 2
 CHAMBER CHAMBER
 HV4_1 HV4_2

0:031 0:031
 11 12
 [2:121] [2:122]

CRYO VALVE
 4 CLOSE
 TIMER
 DV4CLFLT

TON
 TIMER ON DELAY (EN)
 TIMER: T4:134
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:134.DN - | | - File #5 FAULTS - 124

Rung #124

FAULT DWELL 2
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 4 CLOSE CLOSED
 DV4CLFLT HV4S1

T4:134 1:022
 DN 06

CRYO VALVE
 4 CLOSE
 FAULT
 CV4CLFLT
 83
 154

[123]

83/154 - | | - File #5 FAULTS - 141

- () - File #5 FAULTS - 124

630

Rung #125

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 HEATER 2 HEATER 2
 CHAMBER CHAMBER
 HV5_1 HV5_2

0:031 0:031
 13 14
 (2:123) (2:124)

CRYO VALVE
 5 CLOSE
 TIMER
 CV5CLTRM

TON
 TIMER ON DELAY (EN)
 TIMER: T4:135
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:135.DN - | | - File #5 FAULTS - 126

Rung #126

FAULT HEATER 3
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 5 CLOSE CLOSED
 CV5CLTRM HV5S1

T4:135 I:024
 DN 00
 (125)

CRYO VALVE
 5 CLOSE
 FAULT
 CV5CLFLT
 83

()
 155

83/155 - | | - File #5 FAULTS - 141

() - File #5 FAULTS - 126

Rung #127

YO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 3 DWELL 3
 CHAMBER CHAMBER
 HV6_1 HV6_2

0:031 0:031
 15 16
 (2:125) (2:126)

CRYO VALVE
 6 CLOSE
 TIMER
 CV6CLTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:136
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:136.DN - | | - File #5 FAULTS - 128

Rung #128

FAULT DWELL 3
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 6 CLOSE CLOSED
 CV6CLTMR HV6S1

T4:136 I:024
 DN 03

CRYO VALVE
 6 CLOSE
 FAULT
 CV6CLFLT
 83

()
 156

(27)

,156 - | | - File #5 FAULTS - 141

() - File #5 FAULTS - 128

631

Rung #129

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 4 DWELL 4
 CHAMBER CHAMBER
 HV7_1 HV7_2

0:045 0:045
 11 12
 (2:127) (2:128)

CRYO VALVE
 7 CLOSE
 TIMER
 CV7CLTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:137
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:137.DN - | | - File #5 FAULTS - 130

Rung #130

FAULT DWELL 4
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 7 CLOSE CLOSED
 CV7CLTMR HV7S1

T4:137 1:036
 DN 06

CRYO VALVE
 7 CLOSE
 FAULT
 DV7CLFLT
 83

(129)

83/157 - | | - File #5 FAULTS - 141

-() - File #5 FAULTS - 130

Rung #131

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 BUFFER 3 BUFFER 3
 CHAMBER CHAMBER
 HV8_1 HV8_2

0:045 0:045
 13 14
 (2:129) (2:130)

CRYO VALVE
 8 CLOSE
 TIMER
 CV8CLTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:138
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:138.DN - | | - File #5 FAULTS - 132

Rung #132

FAULT BUFFER 3
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 8 CLOSE CLOSED
 CV8CLTMR HV8S1

T4:138 1:040
 DN 00

CRYO VALVE
 8 CLOSE
 FAULT
 CV8CLFLT
 83

(31)

83/158 - | | - File #5 FAULTS - 141

-() - File #5 FAULTS - 132

632

Rung #133

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 5 DWELL 5
 CHAMBER CHAMBER
 HV9_1 HV9_2

0:045 0:045
 15 16
 (2:131) (2:132)

CRYO VALVE
 9 CLOSE
 TIMER
 CV9CLTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:139
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:139.DN - | | - File #5 FAULTS - 134

Rung #134

FAULT DWELL 5
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 9 CLOSE CLOSED
 CV9CLTMR HV9S1

T4:139 1:040
 DN 03

CRYO VALVE
 9 CLOSE
 FAULT
 CV9CLFLT

83
 ()
 159

[133]

83/159 - | | - File #5 FAULTS - 141

- () - File #5 FAULTS - 134

Rung #135

CRYO GATE CRYO GATE
 SOLENOID 1 SOLENOID 2
 DWELL 6 DWELL 6
 CHAMBER CHAMBER
 HV10_1 HV10_2

0:061 0:061
 11 12
 (2:133) (2:134)

CRYO VALVE
 10 CLOSE
 TIMER
 CV10CLTMR

TON
 TIMER ON DELAY (EN)
 TIMER: T4:140
 BASE (SEC): 1.0 (DN)
 PRESET: 5
 ACCUM: 0

T4:140.DN - | | - File #5 FAULTS - 136

Rung #136

FAULT DWELL 6
 DETECT CHAMBER
 CRYO VALVE GATE VALVE
 10 CLOSE CLOSED
 CV10CLTMR HV10S1

T4:140 1:052
 DN 06

CRYO VALVE
 10 CLOSE
 FAULT
 CV10CLFLT

83
 ()
 160

[135]

83/160 - | | - File #5 FAULTS - 141

- () - File #5 FAULTS - 136

633

Rung #137

CRYO GATE CRYO GATE
SOLENOID 1 SOLENOID 2
BUFFER 4 BUFFER 4
CHAMBER CHAMBER
HV11_1 HV11_2
0:061 0:061
13 14
(2:135) (2:136)

CRYO VALVE
11 CLOSE
TIMER
CV11CLTMR

TIMER ON DELAY (EN)
TIMER: T4:141
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCU: 0

T4:141.DN - | | - File #5 FAULTS - 138

Rung #138

FAULT BUFFER 4
DETECT CHAMBER
CRYO VALVE GATE VALVE
11 CLOSE CLOSED
CV11CLTMR HV11S1
T4:141 1:054
DN 00

CRYO VALVE
11 CLOSE
FAULT
CV11CLFLT
83

[137]

B3/161 - | | - File #5 FAULTS - 141

- () - File #5 FAULTS - 138

Rung #139

CRYO GATE CRYO GATE
SOLENOID 1 SOLENOID 2
EXBUFFER EXBUFFER
CHAMBER CHAMBER
HV12_1 HV12_2
0:061 0:061
15 16
(2:137) (2:138)

CRYO VALVE
12 CLOSE
TIMER
CV12CLTMR

TIMER ON DELAY (EN)
TIMER: T4:142
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCU: 0

T4:142.DN - | | - File #5 FAULTS - 140

Rung #140

FAULT EXITLOCK
DETECT CHAMBER
CRYO VALVE GATE VALVE
12 CLOSE CLOSED
CV12CLTMR HV12S1
T4:142 1:054
DN 03

CRYO VALVE
12 CLOSE
FAULT
CV12CLFLT
83

[139]

B3/162 - | | - File #5 FAULTS - 141

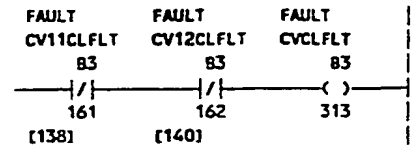
- () - File #5 FAULTS - 140

Rung #141

CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE	CRYO VALVE
1 CLOSE	2 CLOSE	3 CLOSED	4 CLOSE	5 CLOSE	6 CLOSE	7 CLOSE	8 CLOSE	9 CLOSE	10 CLOSE
FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT	FAULT
CV1CLFLT	CV2CLFLT	CV3CLFLT	CV4CLFLT	CV5CLFLT	CV6CLFLT	CV7CLFLT	CV8CLFLT	CV9CLFLT	CV10CLFLT
83	83	83	83	83	83	83	83	83	83
151	152	153	154	155	156	157	158	159	160
[118]	[120]	[122]	[124]	[126]	[128]	[130]	[132]	[134]	[136]

CRYO VALVE CRYO VALVE CRYO VALVE
11 CLOSE 12 CLOSE CLOSE

634

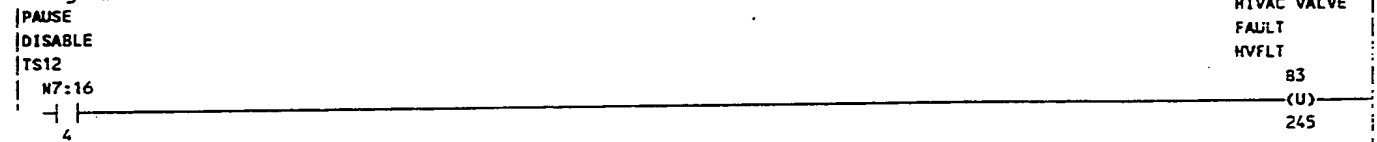


83/313 - \neg / \neg - File #5 FAULTS - 142
 - () - File #5 FAULTS - 141

Rung #142

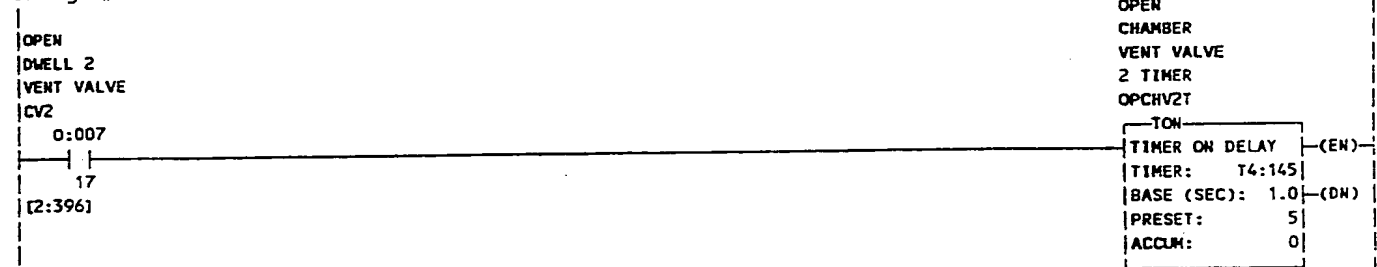


Rung #143



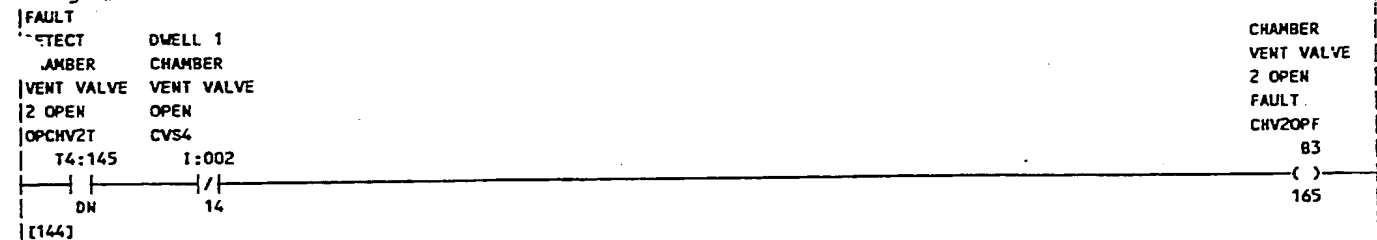
[2:3]
 83/245 - \neg / \neg - File #2 MAIN_PRGRM - 625
 - (L) - File #5 FAULTS - 142
 - (U) - File #5 FAULTS - 143

Rung #144



T4:145.DN - \neg / \neg - File #5 FAULTS - 145

Rung #145



83/165 - \neg / \neg - File #5 FAULTS - 156
 - () - File #5 FAULTS - 145

635

Rung #146

OPEN
DWELL 2
VENT VALVE
CV2

0:007

/

17

[2:396]

CLOSE
CHAMBER
VENT VALVE
2 TIMER
CLCHV2T

TON
TIMER ON DELAY
TIMER: T4:146
BASE (SEC): 1.0
PRESET: 5
ACCUM: 5

T4:146.DN - / - File #5 FAULTS - 147

Rung #147

FAULT
DETECT DWELL 1
CHAMBER CHAMBER
VENT VALVE VENT VALVE
2 CLOSE CLOSED
CLCHV2T CVS3

T4:146

1:002

/

DN

13

[146]

B3/166 - / - File #5 FAULTS - 156

- () - File #5 FAULTS - 147

ng #148

OPEN
DWELL 3
VENT VALVE
CV3

0:027

/

16

[2:401]

OPEN
CHAMBER
VENT VALVE
3 TIMER
OPCHV3T

TON
TIMER ON DELAY
TIMER: T4:147
BASE (SEC): 1.0
PRESET: 5
ACCUM: 0

T4:147.DN - / - File #5 FAULTS - 149

Rung #149

FAULT
DETECT DWELL 3
CHAMBER CHAMBER
VENT VALVE VENT VALVE
3 OPEN OPEN
OPCHV3T CVS6

T4:147

1:022

/

DN

12

[148]

B3/167 - / - File #5 FAULTS - 156

- () - File #5 FAULTS - 149

CHAMBER
VENT VALVE
3 OPEN
FAULT
CHV3OPF

B3

()

167

636

Rung #150

OPEN
DWELL 3
VENT VALVE
CV3

0:027
16
[2:401]

CLOSE
CHAMBER
VENT VALVE
3 TIMER
CLCHV3T

TON
TIMER ON DELAY
TIMER: T4:148
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 5

T4:148.DN - | | - File #5 FAULTS - 151

Rung #151

FAULT
DETECT DWELL 4
CHAMBER CHAMBER
VENT VALVE VENT VALVE
3 CLOSE CLOSED
CLCHV3T CV55

T4:148 1:022
DN 11

CHAMBER
VENT VALVE
3 CLOSE
FAULT
CHV3CLF
83

168

[150]

83/168 - | | - File #5 FAULTS - 156

- () - File #5 FAULTS - 151

ng #152

OPEN
DWELL 5
VENT VALVE
CV4

0:043
16
[2:403]

OPEN
CHAMBER
VENT VALVE
4 TIMER
OPCHV4T

TON
TIMER ON DELAY
TIMER: T4:149
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCUM: 0

T4:149.DN - | | - File #5 FAULTS - 153

Rung #153

FAULT
DETECT DWELL 5
CHAMBER CHAMBER
VENT VALVE VENT VALVE
4 OPEN OPEN
OPCHV4T CV58

T4:149 1:036
DN 12

CHAMBER
VENT VALVE
4 OPEN
FAULT
CHV4OPF
83

169

[152]

83/169 - | | - File #5 FAULTS - 156

- () - File #5 FAULTS - 153

637

Rung #154

| OPEN
| DWELL 5
| VENT VALVE
| CV4

0:043

| / |
| 16

[2:403]

CLOSE
CHAMBER
VENT VALVE
4 TIMER
CLCHV4T

TON

| TIMER ON DELAY | (EN)
| TIMER: T4:150 |
| BASE (SEC): 1.0 | (ON)
| PRESET: 5 |
| ACCUM: 5 |

T4:150.DN - | | - File #5 FAULTS - 155

Rung #155

| FAULT
| DETECT DWELL 5
| CHAMBER CHAMBER
| VENT VALVE VENT VALVE
| 4 CLOSE CLOSED
| CLCHV4T CVS7

T4:150 1:036

| / |
| DN 11

CHAMBER
VENT VALVE
4 CLOSE
FAULT
CHV4CLF

83

()

170

[154]

83/170 - | / | - File #5 FAULTS - 156

- () - File #5 FAULTS - 155

ng #156

| CHAMBER CHAMBER CHAMBER CHAMBER CHAMBER CHAMBER
| VENT VALVE VENT VALVE VENT VALVE VENT VALVE VENT VALVE
| 2 OPEN 2 CLOSE 3 OPEN 3 CLOSE 4 OPEN 4 CLOSE
| FAULT FAULT FAULT FAULT FAULT FAULT
| CHV2OPF CHV2CLF CHV3OPF CHV3CLF CHV4OPF CHV4CLF

| 83 83 83 83 83 83
| / / / / / /
| 165 166 167 168 169 170

CHAMBER
VENT VALVE
NO FAULT
CHVNF

83

()

173

[145] [147] [149] [151] [153] [155]

83/173 - | / | - File #5 FAULTS - 157

- () - File #5 FAULTS - 156

Rung #157

| CHAMBER
| VENT VALVE
| NO FAULT
| CHVNF

83

| / |
| 173

CHAMBER
VENT VALVE
FAULT
CHVF

83

()

174

[156]

83/174 - | | - File #2 MAIN_PRGRM - 625

- (L) - File #5 FAULTS - 157

- (U) - File #5 FAULTS - 158

Rung #158

| PAUSE
| DISABLE
| TS12

N7:16

| / |
| 4

[2:31]

CHAMBER
VENT VALVE
FAULT
CHVF

83

(U)

174

83/174 - | | - File #2 MAIN_PRGRM - 625

- (L) - File #5 FAULTS - 157

638

-(U)- - File #5 FAULTS - 158

Rung #159

OPEN
LOAD LOCK
ROUGH
VALVE
RV1

0:010

11

[2:167]

OPEN
ROUGH VENT
VALVE 1
TIMER
OPRV1T

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:153
BASE (SEC):	1.0 (DN)
PRESET:	23
ACCUM:	0

T4:153.DN - | | - File #5 FAULTS - 160

Rung #160

FAULT LLOCK
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 1 VALVE
OPEN OPEN
OPRV1T RVS2

T4:153 1:002

DN

16

[159]

ROUGH VALVE 1
OPEN FAULT
RV1OPF

B3

126

R3/126 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 160

Rung #161

OPEN
LOAD LOCK
ROUGH
VALVE
RV1

0:010

11

[2:167]

CLOSE
ROUGH VENT
VALVE 1
TIMER
CLRVT

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:154
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	4

T4:154.DN - | | - File #5 FAULTS - 162

Rung #162

FAULT LLOCK
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 1 VALVE
CLOSE CLOSED
CLRVT RVS1

T4:154 1:002

DN

15

[161]

ROUGH
VALVE 1
CLOSE
FAULT
RV1CLF

B3

127

B3/127 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 162

639

Rung #163

OPEN
DWELL 2
ROUGH
VALVE
RV2

0:030

11

[2:56]

OPEN
ROUGH VENT
VALVE 2
TIMER
OPRV2T

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:155
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	0

T4:155.DN - | | - File #5 FAULTS - 164

Rung #164

FAULT DWELL 2
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 2 VALVE
OPEN OPEN
OPRV2T RVS4

T4:155 1:022

DN

16

[163]

ROUGH VALVE 2
OPEN FAULT
RV2OPF

83

128

83/128 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 164

ng #165

OPEN
DWELL 2
ROUGH
VALVE
RV2

0:030

11

[2:56]

CLOSE
ROUGH VENT
VALVE 2
TIMER
CLRVT

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:156
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	5

T4:156.DN - | | - File #5 FAULTS - 166

Rung #166

FAULT DWELL 2
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 2 VALVE RV2
CLOSE CLOSED
CLRVT RVS3

T4:156 1:022

DN

15

[165]

ROUGH VALVE 2
CLOSE FAULT
RV2CLF

83

129

83/129 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 166

640

Rung #167

OPEN
DWELL 4
ROUGH
VALVE
RV3

0:044

11

[2:57]

OPEN
ROUGH VENT
VALVE 3
TIMER
OPRV3T

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:157
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	0

T4:157.DN - | | - File #5 FAULTS - 168

Rung #168

FAULT DWELL 4
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 3 VALVE
OPEN OPEN
OPRV3T RVS6

T4:157

I:036

DN

16

[167]

83/130 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 168

Rung #169

OPEN
DWELL 4
ROUGH
VALVE
RV3

0:044

11

[2:57]

CLOSE
ROUGH VENT
VALVE 1
TIMER
CLR3T

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:158
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	5

T4:158.DN - | | - File #5 FAULTS - 170

Rung #170

FAULT DWELL 4
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 3 VALVE
CLOSE CLOSED
CLR3T RV55

T4:158

I:036

DN

15

[169]

83/131 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 170

ROUGH VALVE 3
CLOSE FAULT
RV3CLF

83

()

131

641

Rung #171

OPEN
DWELL 6
ROUGH
VALVE
RV4

0:060

11

[2:58]

OPEN
ROUGH VENT
VALVE 4
TIMER
OPRV4T

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:159
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	0

T4:159.DN - | | - File #5 FAULTS - 172

Rung #172

DWELL 5
FAULT CHAMBER
DETECT ROUGH
ROUGH VENT VALVE
VALVE 4 OPEN
OPRV4T RVS8

T4:159

I:052

DN

15

ROUGH VALVE 4
OPEN FAULT
RV4OPF

83

132

[171]

83/132 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 172

ung #173

OPEN
DWELL 6
ROUGH
VALVE
RV4

0:060

11

[2:58]

CLOSE
ROUGH VENT
VALVE 4
TIMER
CLR4T

TON	
TIMER ON DELAY	(EN)
TIMER:	T4:160
BASE (SEC):	1.0 (DN)
PRESET:	5
ACCUM:	5

T4:160.DN - | | - File #5 FAULTS - 174

Rung #174

FAULT DWELL 5
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 4 VALVE
CLOSE CLOSED
CLR4T RVS7

T4:160

I:052

DN

14

ROUGH VALVE 4
CLOSE FAULT
RV4CLF

83

133

[173]

83/133 - | | - File #5 FAULTS - 179

-() - File #5 FAULTS - 174

642

Rung #175

OPEN
EXLOCK
ROUGH
VALVE
RV5

O:060

12

(2:340)

OPEN
ROUGH VENT
VALVE 5
TIMER
OPRVST

TON
TIMER ON DELAY (EN)
TIMER: T4:161
BASE (SEC): 1.0 (DN)
PRESET: 60
ACCU: 0

T4:161.DN - | | - File #5 FAULTS - 176

Rung #176

FAULT EXLOCK
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 5 VALVE
OPEN OPEN
OPRVST RVS10

T4:161

I:052

DN

17

ROUGH VALVE 5
OPEN FAULT
RV5OPF

B3

()

134

[175]

B3/134 - | | - File #5 FAULTS - 179

() - File #5 FAULTS - 176

ng #177

OPEN
EXLOCK
ROUGH
VALVE
RV5

O:060

12

(2:340)

CLOSE
ROUGH VENT
VALVE 5
TIMER
CLRVST

TON
TIMER ON DELAY (EN)
TIMER: T4:162
BASE (SEC): 1.0 (DN)
PRESET: 5
ACCU: 5

T4:162.DN - | | - File #5 FAULTS - 178

Rung #178

FAULT EXLOCK
DETECT CHAMBER
ROUGH VENT ROUGH
VALVE 5 VALVE
CLOSE CLOSED
CLRVST RVS9

T4:162

I:052

DN

16

ROUGH VALVE 5
CLOSE FAULT
RV5CLF

B3

()

135

[177]

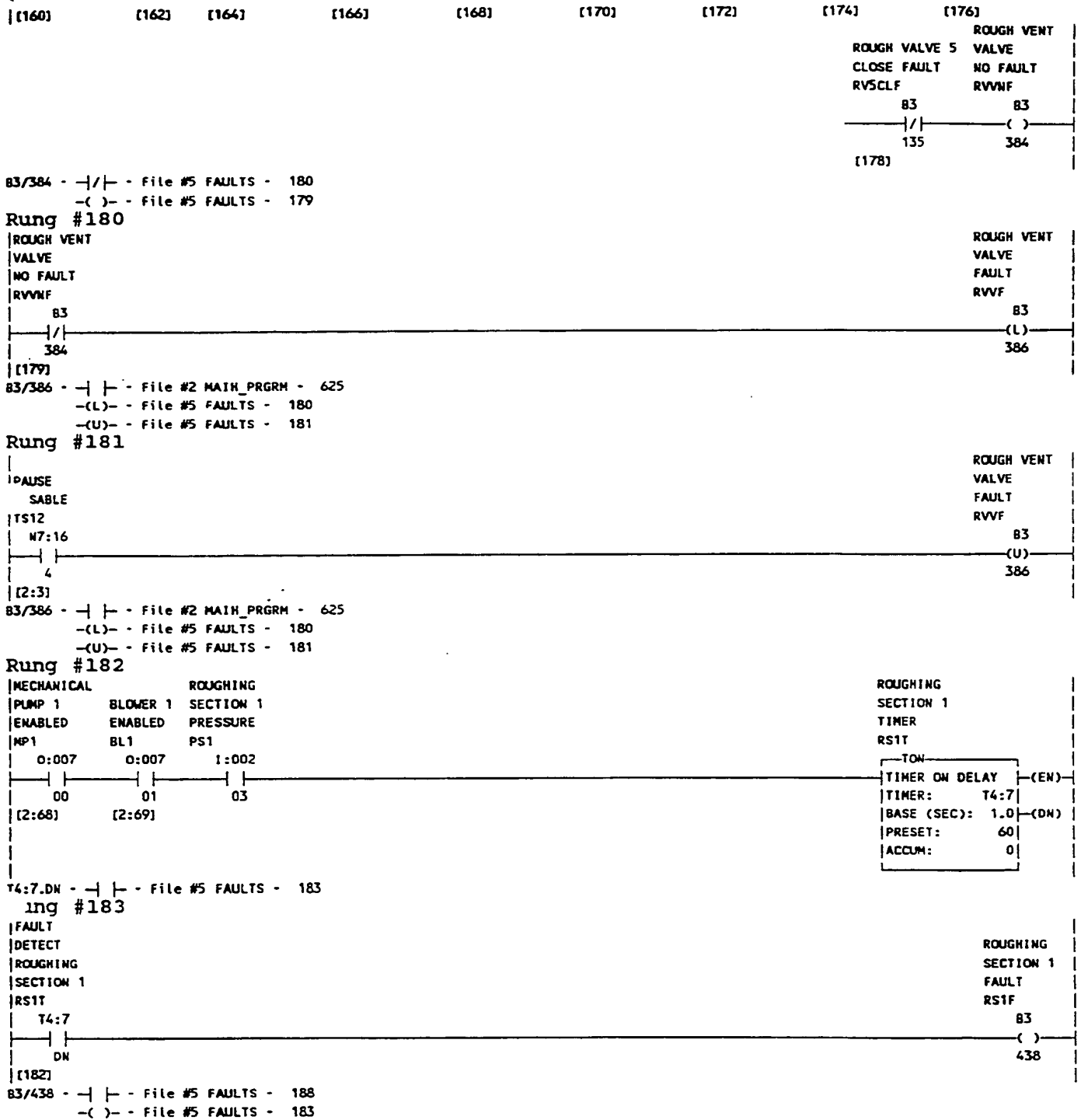
B3/135 - | | - File #5 FAULTS - 179

() - File #5 FAULTS - 178

Rung #179

ROUGH VALVE 1		ROUGH VALVE 2		ROUGH VALVE 2		ROUGH VALVE 3		ROUGH VALVE 3		ROUGH VALVE 4		ROUGH VALVE 4		ROUGH VALVE 5	
ROUGH VALVE 1	CLOSE	ROUGH VALVE 2	OPEN FAULT	ROUGH VALVE 2	CLOSE FAULT	ROUGH VALVE 3	OPEN FAULT	ROUGH VALVE 3	CLOSE FAULT	ROUGH VALVE 4	OPEN FAULT	ROUGH VALVE 4	CLOSE FAULT	ROUGH VALVE 5	OPEN FAULT
RV1OPF	RV1CLF	RV2OPF	RV2CLF	RV3OPF	RV3CLF	RV4OPF	RV4CLF	RV5OPF							
B3	B3	B3	B3	B3	B3	B3	B3	B3	B3	B3	B3	B3	B3	B3	B3
/	/	/	/	/	/	/	/	/	/	/	/	/	/	/	/
126	127	128	129	130	131	132	133	134							

643



644

Rung #184

MECHANICAL ROUGHING
PUMP 2 BLOWER 2 SECTION 2
ENABLED ENABLED PRESSURE
MP2 BL2 PS8

0:027 0:027 1:022
00 01 05
[2:73] [2:74]

ROUGHING
SECTION 2
TIMER
RS2T

TON
TIMER ON DELAY (EN)
TIMER: T4:8
BASE (SEC): 1.0 (DN)
PRESET: 60
ACCUM: 0

T4:8.DN - | | - File #5 FAULTS - 185

Rung #185

FAULT
DETECT
ROUGHING
SECTION 2
RS2T

ROUGHING
SECTION 2
FAULT
RS2F

T4:8
DN

83
439

[184]

83/439 - | | - File #5 FAULTS - 188
-() - File #5 FAULTS - 185

Rung #186

MECHANICAL ROUGHING
PUMP 3 BLOWER 3 SECTION 3
ENABLED ENABLED PRESSURE
MP3 BL3 PS7

0:057 0:057 1:052
00 01 05
[2:78] [2:79]

ROUGHING
SECTION 3
TIMER
RS3T

TON
TIMER ON DELAY (EN)
TIMER: T4:9
BASE (SEC): 1.0 (DN)
PRESET: 60
ACCUM: 0

T4:9.DN - | | - File #5 FAULTS - 187

Rung #187

FAULT
DETECT
ROUGHING
SECTION 3
RS3T

ROUGHING
SECTION 3
FAULT
RS3F

T4:9
DN

83
440

[186]

83/440 - | | - File #5 FAULTS - 188
-() - File #5 FAULTS - 187

645

Rung #188

ROUGHING
SECTION 1
FAULT
RS1F

83

438

[183]

83/385 - | | - File #2 MAIN_PRGRM - 626
-(U)- - File #5 FAULTS - 189

ROUGHING
SECTION 2
FAULT
RS2F

83

439

[185]

ROUGHING
SECTION 3
FAULT
RS3F

83

440

[187]

.ng #189

PAUSE
DISABLE
TS12
N7:16

4

[2:3]

83/385 - | | - File #2 MAIN_PRGRM - 626
-(L)- - File #5 FAULTS - 188
-(U)- - File #5 FAULTS - 189

Rung #190

HEATER
SHIELD H2O
FLOW
SWITCH 1
HSFS1

I:006

10

HEATER
SHIELD H2O
FLOW
SWITCH 2
HSFS2

I:006

11

83/216 - | | - File #5 FAULTS - 199
-|/| - File #2 MAIN_PRGRM - 213

MECHANICAL
PUMP FAILURE
MECH_P_FAIL

83

(L)

385

MECHANICAL
PUMP FAILURE
MECH_P_FAIL

83

(U)

385

HEATER
SHIELD H2O
FLOW
GROUP 1
FAULT
HSFG1F

83

()

216

Rung #191

HEATER
SHIELD H20
FLOW
SWITCH 3
HSFS3

I:006

12

HEATER
SHIELD H20
FLOW
SWITCH 4
HSFS4

I:006

13

Rung #192

HEATER
SHIELD H20
FLOW
SWITCH 5
HSFS5

I:023

16

HEATER
SHIELD H20
FLOW
SWITCH 6
HSFS6

I:023

17

B3/217 - | | - File #5 FAULTS - 199
| | - File #2 MAIN_PRGRM - 226

B3/218 - | | - File #5 FAULTS - 199

HEATER
SHIELD H20
FLOW
GROUP 2
FAULT
HSFG2F

83

217

HEATER
SHIELD H20
FLOW
GROUP 3
FAULT
HSFG3F

83

218

647

Rung #193

CATHODE
WATER FLOW
SWITCH 1
CHR1A
I:026

|/|
10

B3/136 - | - File #5 FAULTS - 202

CATHODE
WATER FLOW
SWITCH 2
CHR2A
I:026

|/|
11

CATHODE
WATER FLOW
SWITCH 3
CHR3A
I:026

|/|
12

CATHODE
WATER FLOW
SWITCH 4
CHR4A
I:026

|/|
13

CATHODE
SHIELD H2O
FLOW
SWITCH 1
CSFS1
I:025

|/|
04

CATHODE
SHIELD H2O
FLOW
SWITCH 2
CSFS2
I:025

|/|
05

CATHODE
H2O FLOW
SWITCH
GROUP 1
FAULT
CWFSG1F
83

()
136

648

Rung #194

WATER FLOW
SWITCH 5
CHR18

I:026

14

CATHODE
WATER FLOW
SWITCH 6
CHR28

I:026

15

CATHODE
WATER FLOW
SWITCH 7
CHR38

I:026

16

CATHODE
WATER FLOW
SWITCH 8
CHR48

I:026

17

83/137 - - File #5 FAULTS - 202

CATHODE
H2O FLOW
SWITCH
GROUP 2
FAULT
CVFSG2F

83

137

649

Rung #195

CATHODE
WATER FLOW
SWITCH 9
WFS9

I:042

|/|
10

B3/138 - | - File #5 FAULTS - 202

CATHODE
H2O FLOW
SWITCH
GROUP 3
FAULT
CMFSG3F
B3

()
138

CATHODE
WATER FLOW
SWITCH 10
WFS10

I:042

|/|
11

CATHODE
WATER FLOW
SWITCH 11
WFS11

I:042

|/|
12

CATHODE
WATER FLOW
SWITCH 12
WFS12

I:042

|/|
13

CATHODE
SHIELD H2O
FLOW
SWITCH 9
CSFS9

I:041

|/|
04

CATHODE
SHIELD H2O
FLOW
SWITCH 10
CSFS10

I:041

|/|
05

Rung #196

CATHODE
WATER FLOW
SWITCH 13
WFS13

1:042

|/|
14

B3/139 - | - File #5 FAULTS - 202

CATHODE
WATER FLOW
SWITCH 14
WFS14

1:042

|/|
15

CATHODE
WATER FLOW
SWITCH 15
WFS15

1:042

|/|
16

CATHODE
WATER FLOW
ITCH 16

WFS16

1:042

|/|
17

CATHODE
H2O FLOW
SWITCH
GROUP 4
FAULT
CWFSG4F

83

()
139

651

Rung #197

CATHODE
WATER FLOW
SWITCH 17
WFS17
1:056

/|
10

B3/140 - - File #5 FAULTS - 202

CATHODE
WATER FLOW
SWITCH 18
WFS18
1:056

/|
11

CATHODE
WATER FLOW
SWITCH 19
WFS19
1:056

/|
12

CATHODE
WATER FLOW
SWITCH 20
WFS20
1:056

/|
13

CATHODE
SHIELD
H2O FLOW
SWITCH 17
CSFS17
1:055

/|
04

CATHODE
SHIELD
H2O FLOW
SWITCH 18
CSFS18
1:055

/|
05

CATHODE
H2O FLOW
SWITCH
GROUP 5
FAULT
CWFSG5F
B3

()
140

652

Rung #198

CATHODE
WATER FLOW
SWITCH 21
WFS21

I:056

14

CATHODE
H2O FLOW
SWITCH
GROUP 6
FAULT
CWFSG6F
B3

141

B3/141 - - File #5 FAULTS - 202

CATHODE
WATER FLOW
SWITCH 22
WFS22

I:056

15

CATHODE
WATER FLOW
SWITCH 23
WFS23

I:056

16

CATHODE
WATER FLOW
SWITCH 24
WFS24

I:056

17

653

Rung #199

HEATER
SHIELD H20
FLOW
GROUP 1
FAULT
HSFG1F
83
N7:16

PAUSE
DISABLE
TS12

HEATER SHIELD
FLOW FAULT
TIMER
HSFFTMR

TON
TIMER ON DELAY (EW)
TIMER: T4:93
BASE (SEC): 1.0 (DN)
PRESET: 20
ACCUM: 0

216
[190] [2:3]

HEATER
SHIELD H20
FLOW
GROUP 2
FAULT
HSFG2F
83

217
[191]

HEATER
SHIELD H20
FLOW
GROUP 3
FAULT
HSFG3F
83

218
[192]

T4:93.DN - | | - File #2 MAIN_PRGRM - 223
File #5 FAULTS - 200
T4:93.IT - | | - File #2 MAIN_PRGRM - 718

Rung #200

HSFFTMR
T4:93

DN
[199]

B3/219 - | | - File #2 MAIN_PRGRM - 625
-(L)- File #5 FAULTS - 200
-(U)- File #5 FAULTS - 201

Rung #201

PAUSE
DISABLE
TS12
N7:16

4
[2:3]

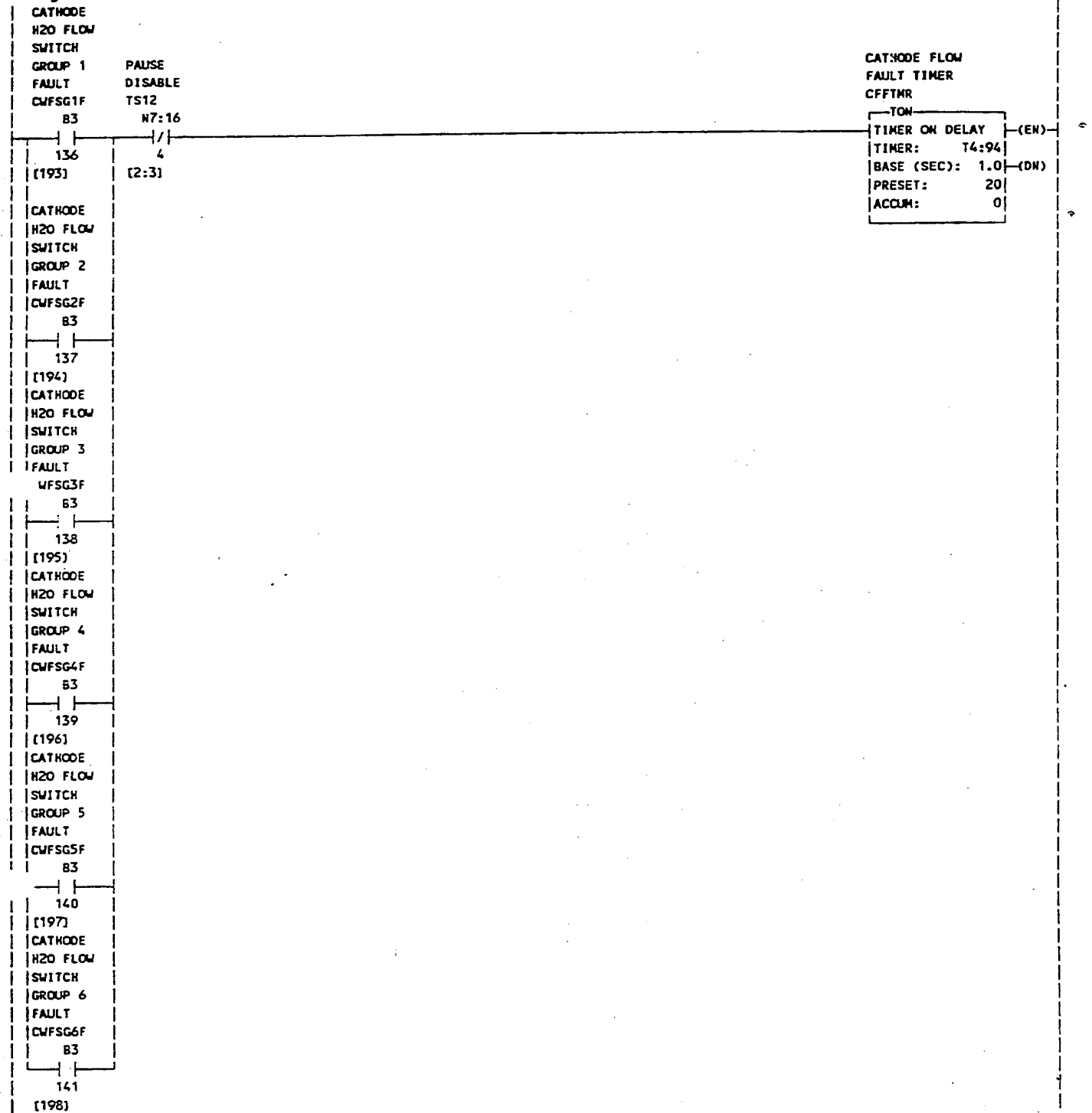
B3/219 - | | - File #2 MAIN_PRGRM - 625
-(L)- File #5 FAULTS - 200
-(U)- File #5 FAULTS - 201

HEATER
SHIELD H20
FLOW FAULT
HSFF
83
(L)
219

HEATER
SHIELD H20
FLOW FAULT
HSFF
83
(U)
219

654

Rung #202



655

T4:94.DN - | | - File #5 FAULTS - 203
 T4:94.TT - | | - File #2 MAIN_PRGRM - 718
 Rung #203

CFFTR

T4:94

DN

[202]

B3/220 - | | - File #2 MAIN_PRGRM - 625
 -(L)- - File #5 FAULTS - 203
 -(U)- - File #5 FAULTS - 204

Rung #204

PAUSE

DISABLE

TS12

N7:16

4

[2:3]

B3/220 - | | - File #2 MAIN_PRGRM - 625
 -(L)- - File #5 FAULTS - 203
 -(U)- - File #5 FAULTS - 204

Rung #205

WI	PIRINI	PIRINI	PIRINI	PIRINI	PIRINI	PIRINI	PIRINI	PIRINI
GUAGE 1	GUAGE 2	GUAGE 3	GUAGE 4	GUAGE 5	GUAGE 6	GUAGE 7	GUAGE 8	GUAGE 8
NO FAULT	NO FAULT	NO FAULT	NO FAULT	NO FAULT	NO FAULT	NO FAULT	NO FAULT	NO FAULT
PGNF1	PGNF2	PGNF3	PGNF4	PGNF5	PGNF6	PGNF7	PGNF8	PGNF8
I:004	I:004	I:024	I:024	I:040	I:040	I:054	I:054	I:054
14	15	14	15	14	15	14	15	15

B3/465 - | | - File #2 MAIN_PRGRM - 23
 -|/ - File #2 MAIN_PRGRM - 22,624
 -() - File #5 FAULTS - 205

Rung #206

CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER
COVER 5	COVER 6	COVER 9	COVER 10	COVER 11	COVER 12
CC5	CC6	CC9	CC10	CC11	CC12
I:025	I:025	I:041	I:041	I:055	I:055
00	01	00	01	00	01

B3/315 - |/| - File #5 FAULTS - 207
 -() - File #5 FAULTS - 206

Rung #207

ALL CHAMBER
 ERS CLOSED

ACCC

B3
 315

[206]

B3/467 - | | - File #2 MAIN_PRGRM - 626
 -(L)- - File #5 FAULTS - 207
 -(U)- - File #5 FAULTS - 208

CATHODE
 H2O FLOW
 FAULT
 CWFF

83

(L)

220

CATHODE
 H2O FLOW
 FAULT
 CWFF

83

(U)

220

PIRINI
 GUAGE NO
 FAULT
 PGNF

83

()

465

ALL CHAMBER
 COVERS CLOSED
 ACCC

83

()

315

CHAMBER
 COVERS
 CLOSED
 CCC

83

(L)

467

656

Rung #208

PAUSE
DISABLE
TS12

N7:16

4

[2:3]

83/467 - | | - File #2 MAIN_PRGRM - 626
-(L)- - File #5 FAULTS - 207
-(U)- - File #5 FAULTS - 208

CHAMBER
COVERS
CLOSED
CCC

B3

(U)

467

Rung #209

RETURN TO MAIN
FROM CRYO_RGN

RET

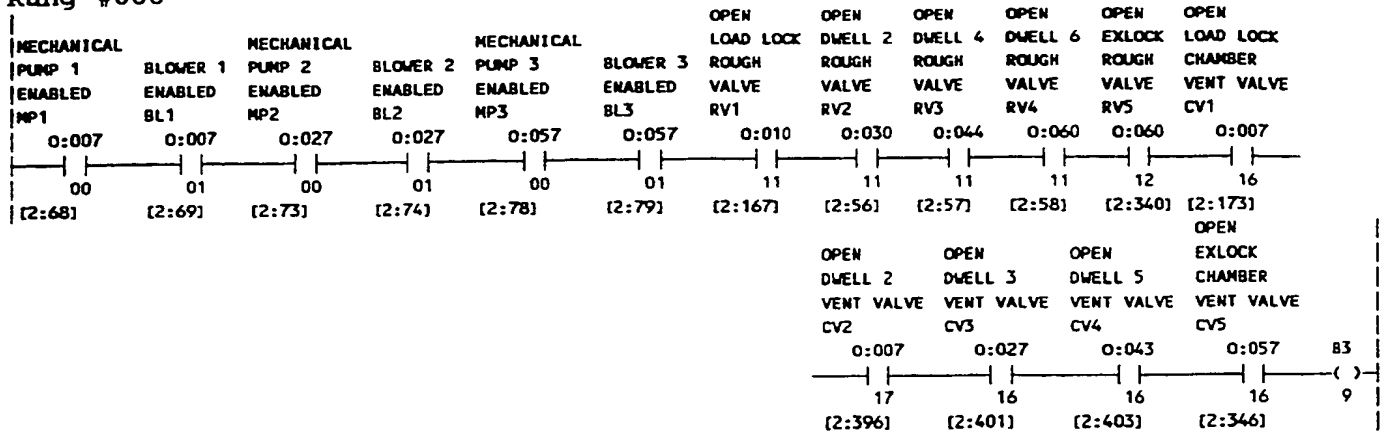
RETURN ()

Rung #210

[END]

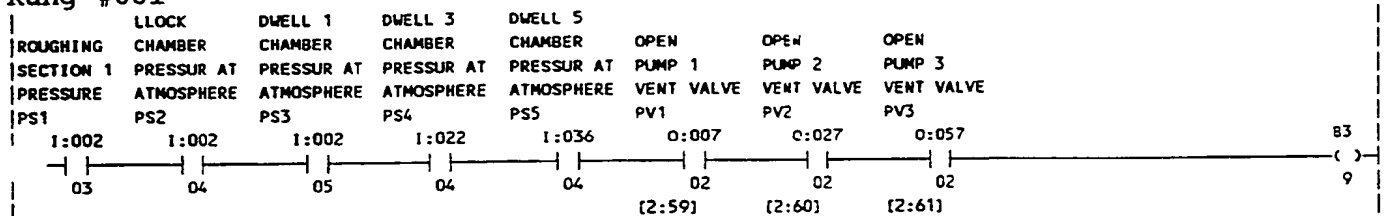
COPYRIGHT 1989, 1990, 1991
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Rung #000



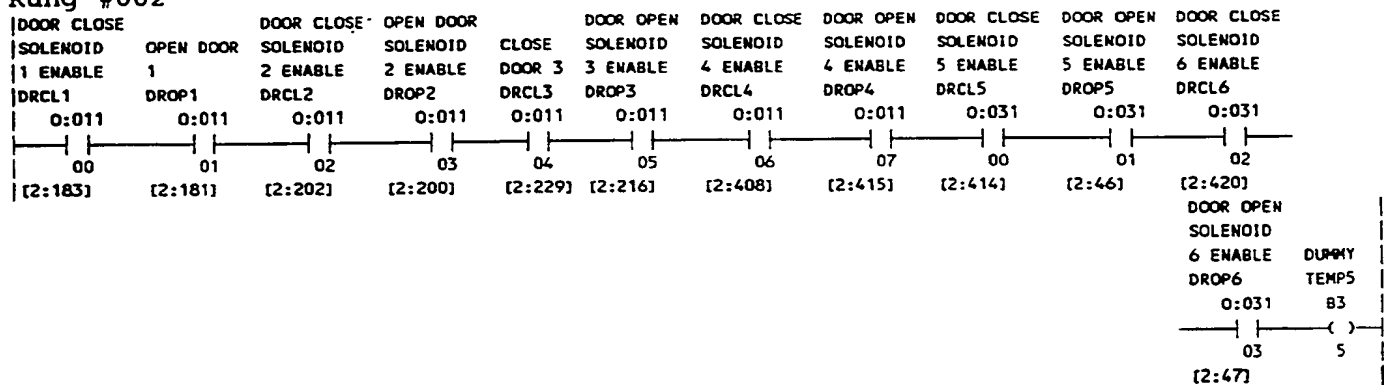
83/9 - () - File #6 TECH_RUNGS - 0,1

Rung #001

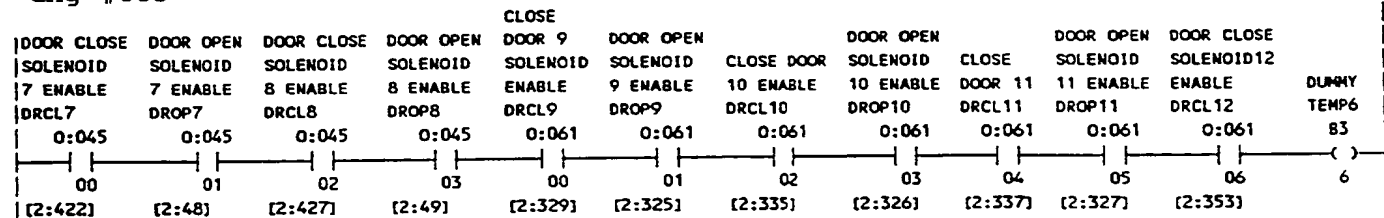


83/9 - () - File #6 TECH_RUNGS - 0

Rung #002



Rung #003



Rung #004

DOOR 1	DOOR 2	DOOR 3	DOOR 4	DOOR 5	DUMMY
OPEN	OPEN	OPEN	OPEN	OPEN	DUMMY
DROP1S	DROP2S	DROP3S	DROP4S	DROP5S	83
1:006	1:006	1:006	1:006	1:026	
01	03	05	07	01	30

83/30 - () - File #6 TECH_RUNGS - 4,8,9,10,11,12,13

Rung #005

Rung #005												TEMP
DOOR 1	DOOR 2	DOOR 3	DOOR 4	DOOR 5	DOOR 6	DOOR 7	DOOR 8	DOOR 9	DOOR 10	DOOR 11	DOOR 12	DURHY_97
CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	CLOSED	83
DRCL1S	DRCL2S	DRCL3S	DRCL4S	DRCL5S	DRCL6S	DRCL7S	DRCL8S	DRCL9S	DRCL10S	DRCL11S	DRCL12S	
1:006	1:006	1:006	1:006	1:026	1:026	1:042	1:042	1:056	1:056	1:056		
00	02	04	06	00	02	00	02	00	02	04	06	97

Rung #006

Run #006

CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE
SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1
HEATER 1	HEATER 2	HEATER 2	DWELL 1	DWELL 1	DWELL 2	DWELL 2	HEATER 2	HEATER 2	DWELL 3	DWELL 3
CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER
HV1	HV2_1	HV2_2	HV3_1	HV3_2	HV4_1	HV4_2	HV5_1	HV5_2	HV6_1	HV6_2

0:011 0:011 0:011 0:011 0:011 0:031 0:031 0:031 0:031 0:031 0:031

11 13 14 15 16 11 12 13 14 15 16

[2:115] [2:117] [2:118] [2:119] [2:120] [2:121] [2:122] [2:123] [2:124] [2:125] [2:126]

CRYO GATE	CHROME	CHROME	MAGNETIC	MAGNETIC	CARBON	CARBON
SOLENOID 1	HI POWER	HI POWER	HI POWER	HI POWER	HI POWER	HI POWER
DWELL 4	SUPPLY 1	SUPPLY 3	SUPPLY 1	SUPPLY 3	SUPPLY 1	SUPPLY 3
CHAMBER	OUTPUT	OUTPUT	OUTPUT	OUTPUT	OUTPUT	OUTPUT
HV7_1	CHRP1	CHRP3	MAGP1	MAGP3	CARP1	CARP3

0:045 0:033 0:033 0:033 0:063 0:063 0:063

11 10 12 14 10 12 14

[2:127] [2:236] [2:242] [2:268] [2:274] [2:299] [2:300]

83 7

B3/7 - -()- - File #6 TECH_RUNGS - 6,7

Rung : #007

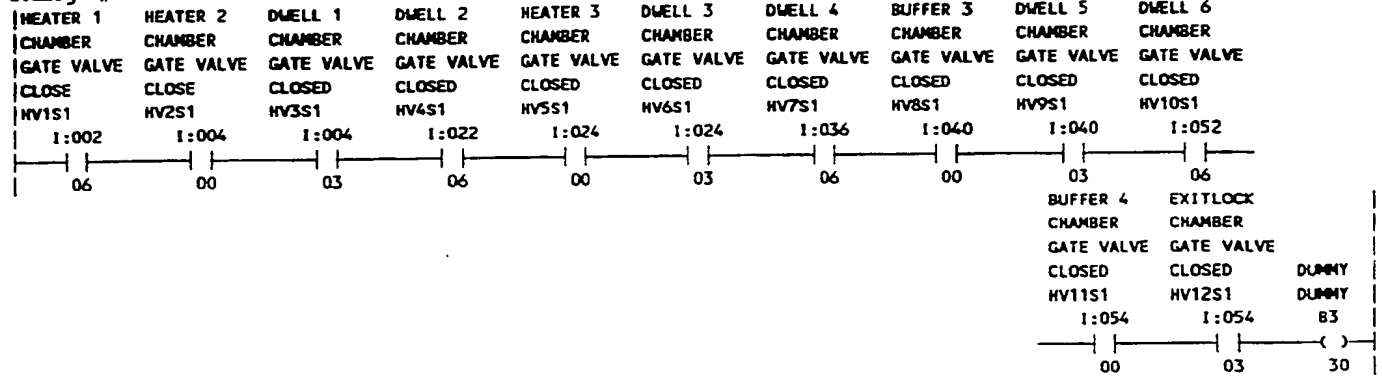
Rung #007

CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE	CRYO GATE
SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1	SOLENOID 2	SOLENOID 1
DWELL 4	BUFFER 3	BUFFER 3	DWELL 5	DWELL 5	DWELL 6	DWELL 6	BUFFER 4	BUFFER 4	EXBUFFER
CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER	CHAMBER
HV7_2	HV8_1	HV8_2	HV9_1	HV9_2	HV10_1	HV10_2	HV11_1	HV11_2	HV12_1
0:045	0:045	0:045	0:045	0:045	0:061	0:061	0:061	0:061	0:061
12	13	14	15	16	11	12	13	14	15
[2:128]	[2:129]	[2:130]	[2:131]	[2:132]	[2:133]	[2:134]	[2:135]	[2:136]	[2:137]

CRYO GATE	OPEN RGA	OPEN RGA	OPEN RGA	OPEN RGA	OPEN RGA	OPEN	OPEN	OPEN	OPEN
SOLENOID 2	ISOLATION	ISOLATION	ISOLATION	ISOLATION	ISOLATION	CAPACITANC	CAPACITANC	CAPACITANC	CAPACITANC
EXBUFFER	VALVE 1	VALVE 2	VALVE 3	VALVE 4	VALVE 1	MANOMETER	MANOMETER	MANOMETER	MANOMETER
CHAMBER	RGAV1	RGAV2	RGAV3	RGAV4	CHV1	ISOLATION	ISOLATION	ISOLATION	ISOLATION
HV12_2					CHV2	VALVE 2	VALVE 3	VALVE 4	CHV4
0:061	0:010	0:030	0:044	0:060	0:010	0:030	0:044	0:060	0:060
16	13	13	13	13	06	06	06	06	12
[2:138]	[2:371]	[2:372]	[2:373]	[2:374]	[2:375]	[2:376]	[2:377]	[2:378]	[2:128]

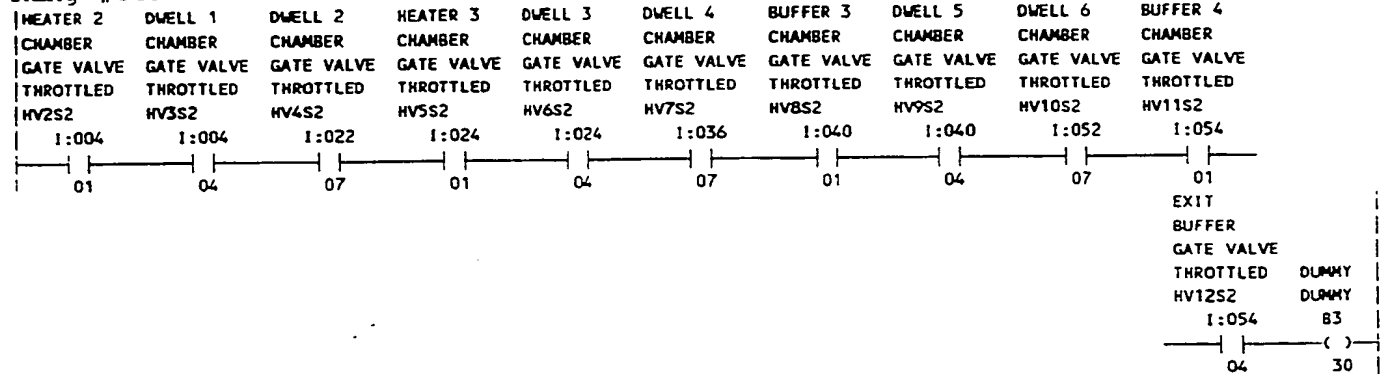
B3/7 - -()- - File #6 TECH_RUNGS - 6

Rung #008



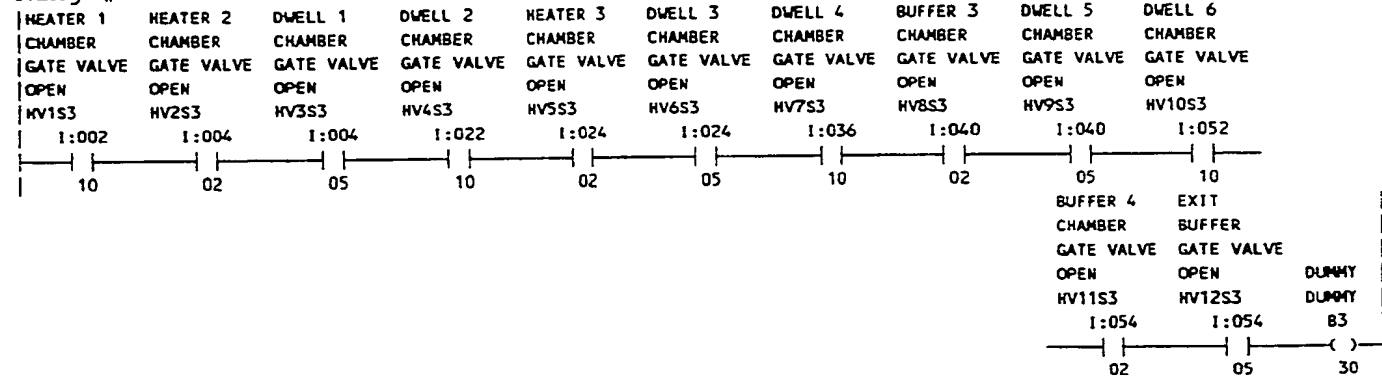
83/30 - () - File #6 TECH_RUNGS - 4,9,10,11,12,13

Rung #009



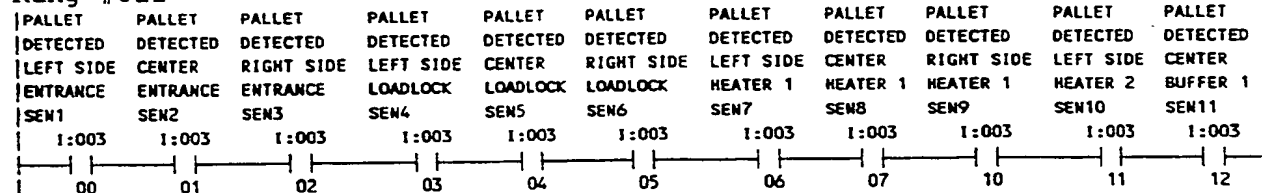
83/30 - () - File #6 TECH_RUNGS - 4,8,10,11,12,13

Rung #010

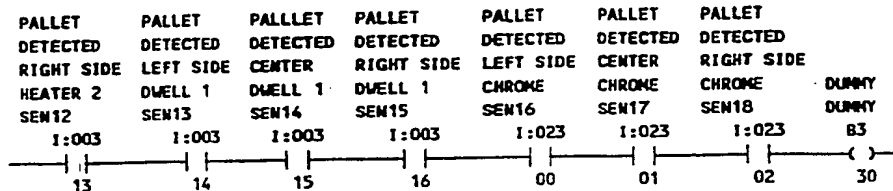


83/30 - () - File #6 TECH_RUNGS - 4,8,9,11,12,13

Rung #011

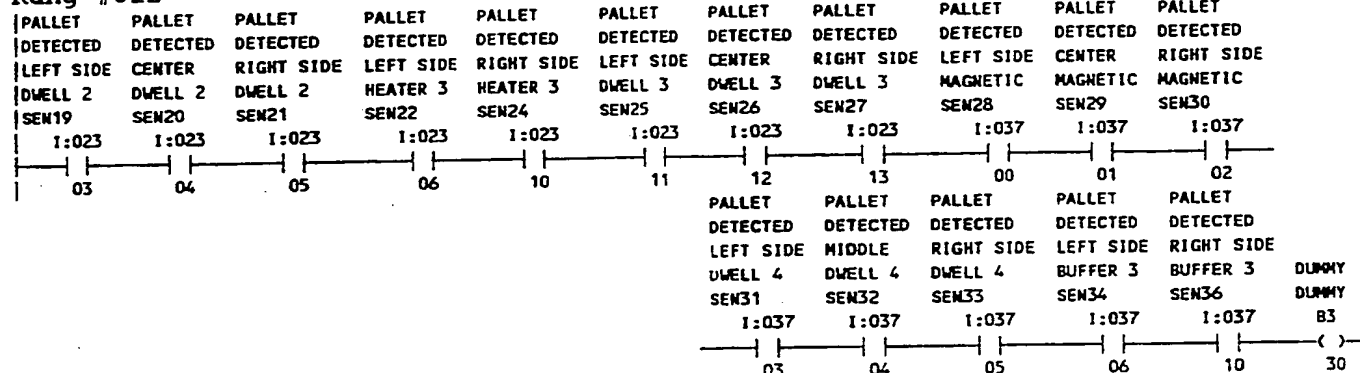


660



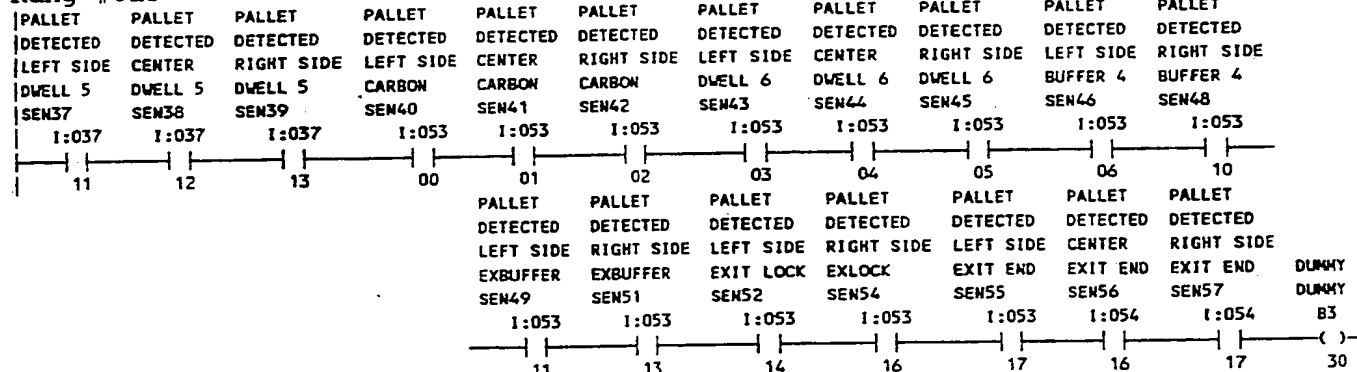
83/30 - () - File #6 TECH_RUNGS - 4,8,9,10,12,13

Rung #012



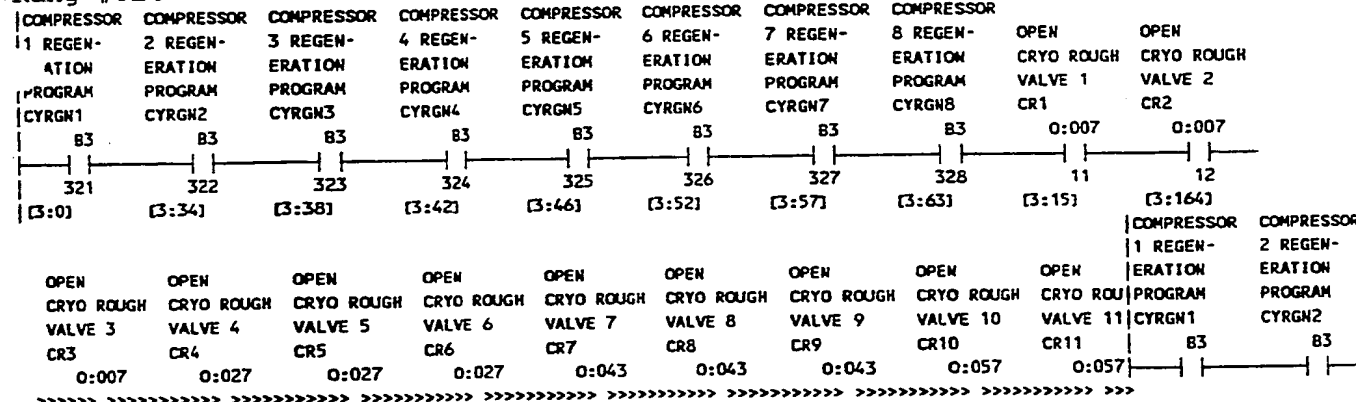
80 - () - File #6 TECH_RUNGS - 4,8,9,10,11,13

Rung #013



83/30 - () - File #6 TECH_RUNGS - 4,8,9,10,11,12

Rung #014



83/15 - () - File #6 TECH_RUNGS - 14,15,17
Rung #015

PURGE 1	PURGE 2	PURGE 3	PURGE 4	PURGE 5	PURGE 6	PURGE 7	PURGE 8	PGC1	PGC2	PGC3	PGC4	PGC5	PGC6	PGC7
P1	P2	P3	P4	P5	P6	P7	P8	T4:21	T4:22	T4:23	T4:24	T4:25	T4:26	T4:27
83	83	83	83	83	83	83	83	TT	TT	TT	TT	TT	TT	TT
[3:5]	[3:74]	[3:75]	[3:76]	[3:77]	[3:78]	[3:79]	[3:80]	[3:9]	[3:110]	[3:111]	[3:112]	[3:113]	[3:114]	[3:115]

PURGING TIME 321
PURGING TIME 5 322

MECHANICAL
PUMP 2
ENABLED
PGC8
T4:28
TT

BLOWER 2
ENABLED
BL2
0:027
01

LINE PRESSURE
MADE-TC10
LPM-TC10
83
250

TEMP
TEMP15
83
15

[3:116] [2:73] [2:74] [2:671]

83/15 - () - File #6 TECH_RUNGS - 14,17
Rung #016

OPEN PURGE VALVE 1	OPEN PURGE VALVE 2	OPEN PURGE VALVE 3	OPEN PURGE VALVE 4	OPEN PURGE VALVE 5	OPEN PURGE VALVE 6	OPEN PURGE VALVE 7	OPEN PURGE VALVE 8	OPEN PURGE VALVE 9	OPEN PURGE VALVE 10
NIF1	NIF2	NIF3	NIF4	NIF5	NIF6	NIF7	NIF8	NIF9	NIF10
0:007	0:007	0:007	0:027	0:027	0:027	0:043	0:043	0:043	0:057
06	07	10	06	07	10	06	07	10	06
[3:7]	[3:88]	[3:89]	[3:91]	[3:90]	[3:92]	[3:93]	[3:94]	[3:95]	[3:96]

CRYO RE-GENERATION FAULT
CRYO RE-GENERATION FAULT
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CRYO RE-GENERATION FAULT
CRYO RE-GENERATION FAULT

OPEN PURGE VALVE 11	OPEN PURGE VALVE 12	COMPRESSOR 1	COMPRESSOR 2	COMPRESSOR 3	COMPRESSOR 4	COMPRESSOR 5	COMPRESSOR 6	COMPRESSOR 7	COMPRESSOR 8	OPEN PURGE VALVE 1	OPEN PURGE VALVE 2
NIF11	NIF12	CRFLT1	CRFLT2	CRFLT3	CRFLT4	CRFLT5	CRFLT6	CRFLT7	CRFLT8	NIF1	NIF2
0:057	0:057	83	83	83	83	83	83	83	83	0:007	0:007
07	10	331	332	333	334	335	336	337	338	06	07
[3:98]	[3:97]	[3:30]	[3:252]	[3:253]	[3:254]	[3:255]	[3:256]	[3:257]	[3:258]	[3:7]	[3:88]

Rung #017

ROUGHING AND ROR 1	ROUGHING AND ROR 2	ROUGHING AND ROR 3	ROUGHING AND ROR 4	ROUGHING AND ROR 5	ROUGHING AND ROR 6	ROUGHING AND ROR 7	ROUGHING AND ROR 8	COMPRESSOR 1	COMPRESSOR 2	COMPRESSOR 3
R&ROR1	R&ROR2	R&ROR3	R&ROR4	R&ROR5	R&ROR6	R&ROR7	R&ROR8	CY1RORL	CY2RORL	CY3RORL
83	83	83	83	83	83	83	83	83	83	83
641	642	643	644	645	646	647	648	601	602	603
[3:11]	[3:128]	[3:129]	[3:130]	[3:131]	[3:132]	[3:133]	[3:134]	[3:16]	[3:175]	[3:177]

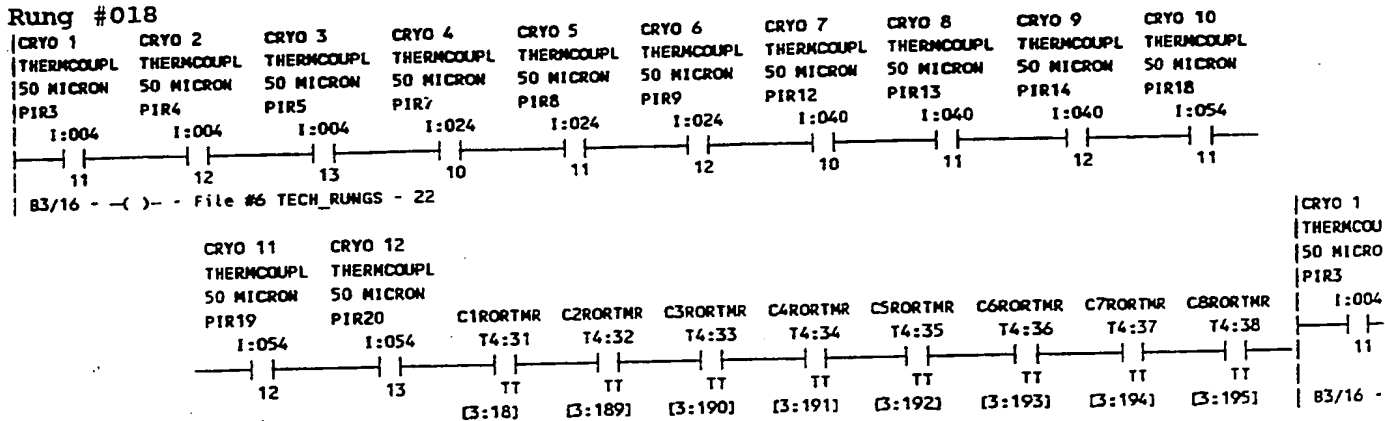
MECHANICAL
PUMP 2
TC=<50
MICRONS
PIR10
1:024
13

COMPRESSOR 4	COMPRESSOR 5	COMPRESSOR 6	COMPRESSOR 7	COMPRESSOR 8	TEMP
ROR LATCH CY4RORL	ROR LATCH CY5RORL	ROR LATCH CY6RORL	ROR LATCH CY7RORL	ROR LATCH CY8RORL	TEMP15
83	83	83	83	83	83
604	605	606	607	608	15
[3:179]	[3:181]	[3:183]	[3:185]	[3:187]	

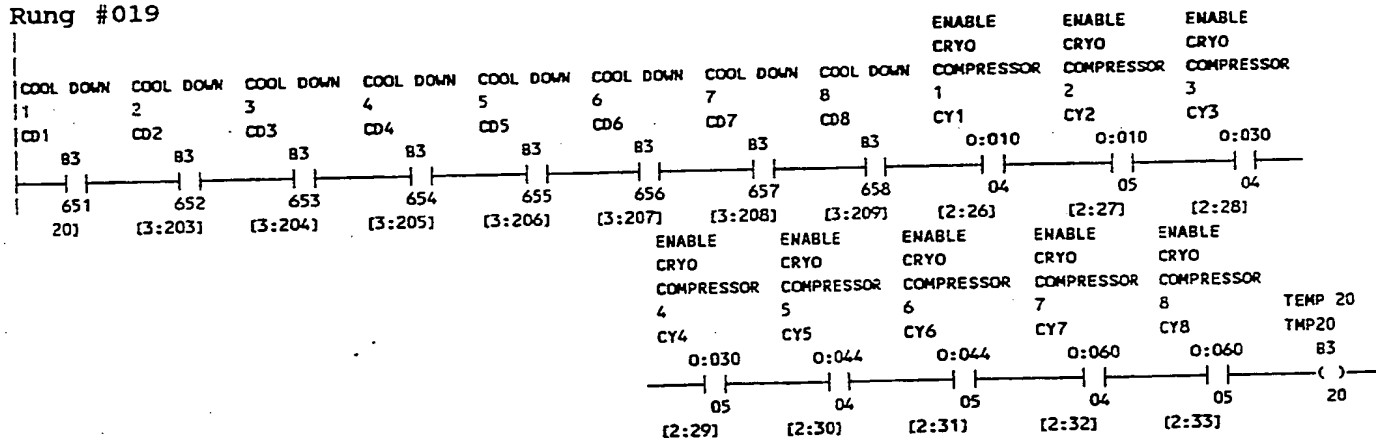
83/15 - () - File #6 TECH_RUNGS - 14,15

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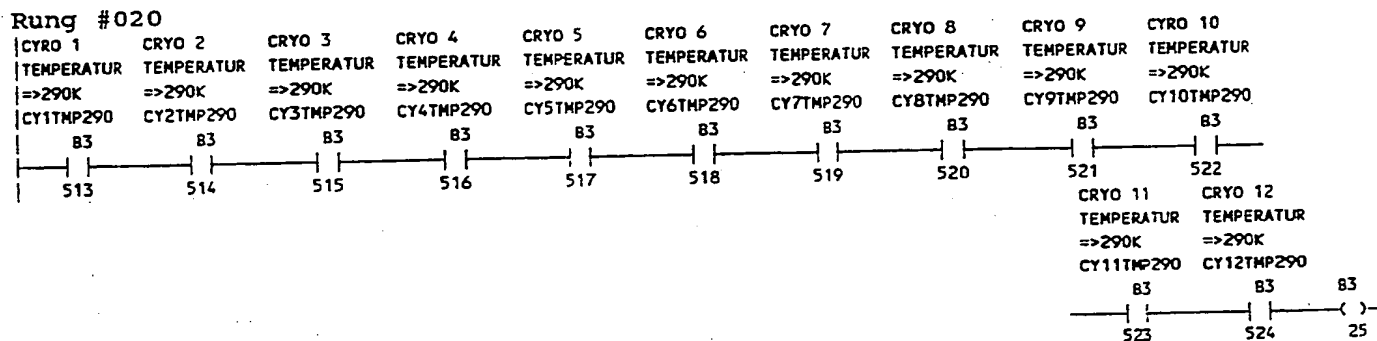
Rung #018



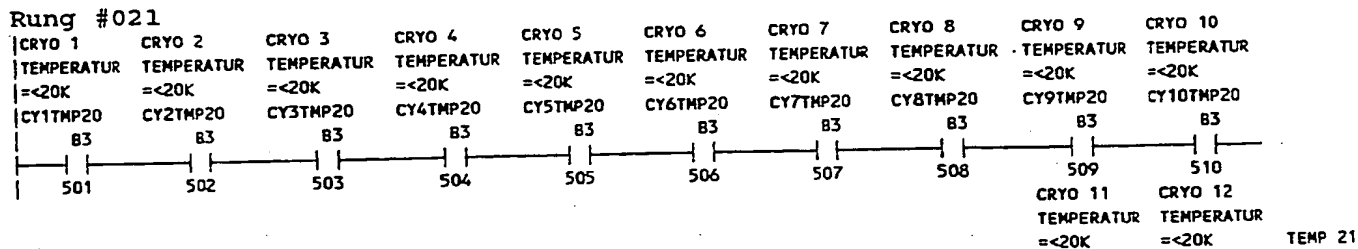
Rung #019



Rung #020



Rung #021



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SECTION N

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WO 92/17621

[illegible]

BNSDOCID: <WO__9217621A1_I_>

TAG	EL	EH	ET	RN	OUTPUT	PSF3	B	C	D	E	F	G	H	NX	CP
ICALC3A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF3		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC4A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF4		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC18	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF1		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC28	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF2		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC38	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF3		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC48	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF4		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC5A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF5		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC6A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF6		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC58	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF5		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC68	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF6		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC7A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF7		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC8A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF8		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC78	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF7		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC88	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF8		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC9A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF9		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC10A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF10		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC11A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF11		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC12A	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF12		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC98	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF9		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC108	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF10		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC118	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF11		0.00	0.00	0.00	0.00	0.00	0.00	.	
ICALC128	0.0	40.0	.	Y	OUTPUT = (A/B)	PSF12		0.00	0.00	0.00	0.00	0.00	0.00	.	
HV1C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		0.00	100.00	HV1S3	1000.0	0.00	0.00	HV1ANA	.
HV2C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV2S2	100.00	HV2S3	1000.0	0.00	0.00	HV2ANA	.
DR1C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR1P1S	1000.0	0.00	0.00	0.00	0.00	DR1ANA	.
HV3C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV3S2	100.00	HV3S3	1000.0	0.00	0.00	HV3ANA	.
HV4C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV4S2	100.00	HV4S3	1000.0	0.00	0.00	HV4ANA	.
HV5C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV5S2	100.00	HV5S3	1000.0	0.00	0.00	HV5ANA	.
HV6C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV6S2	100.00	HV6S3	1000.0	0.00	0.00	HV6ANA	.
DR2C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR2P2S	1000.0	0.00	0.00	0.00	0.00	DR2ANA	.
DR3C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR3P3S	1000.0	0.00	0.00	0.00	0.00	DR3ANA	.
DR4C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR4P4S	1000.0	0.00	0.00	0.00	0.00	DR4ANA	.
DR5C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR5P5S	1000.0	0.00	0.00	0.00	0.00	DR5ANA	.
DR6C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR6P6S	1000.0	0.00	0.00	0.00	0.00	DR6ANA	.
HV7C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV7S2	100.00	HV7S3	1000.0	0.00	0.00	HV7ANA	.
HV8C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV8S2	100.00	HV8S3	1000.0	0.00	0.00	HV8ANA	.
HV9C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV9S2	100.00	HV9S3	1000.0	0.00	0.00	HV9ANA	.
HV10C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV10S2	100.00	HV10S3	1000.0	0.00	0.00	HV10ANA	.
HV12C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))*(E*F)	10.000		HV12S2	100.00	HV12S3	1000.0	0.00	0.00	HV12ANA	.
DR7C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR7P7S	1000.0	0.00	0.00	0.00	0.00	DR7ANA	.
DR8C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR8P8S	1000.0	0.00	0.00	0.00	0.00	DR8ANA	.
DR9C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR9P9S	1000.0	0.00	0.00	0.00	0.00	DR9ANA	.
DR10C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR10P10S	1000.0	0.00	0.00	0.00	0.00	DR10ANA	.
DR11C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR11P11S	1000.0	0.00	0.00	0.00	0.00	DR11ANA	.
DR12C1C	0	32767	.	N	OUTPUT = ((A*B)+(C*D))	10.000		DR12P12S	1000.0	0.00	0.00	0.00	0.00	DR12ANA	.

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JAG	CT	CLO	OT	OP	ST	SC	IS	1	OUTPUT	EQUAL	A_INPUT	B_INPUT	C_INPUT	D_INPUT	E_INPUT	F_INPUT	G	H	DESC			
PSBL1	CLOSE	OPEN	2	ON	(((A*B)+C)*D)*E)*F)				PSON1	PSON2	PSON3	PSON4	PSON5	PSON6	PSON7	PSON8	0	0	Power Supplies on Logic	PSAU101		
PSBL2	CLOSE	OPEN	2	ON	(((A*B)+C)*D)*E)*F)				PSON7	PSON8	PSON9	PSON10	PSON11	PSON12	PSON13	PSON14	0	0	Power Supplies on Logic	PSAU102		
PSF11	CLOSE	OPEN	2:1	ON	(((A*B)+C)*D)*E)*F)				CHR1A	CHR2A	CHR3A	CHR4A	CHR51	CHR52	CHR53	CHR54	0	0	Water Flow Interlocks: PS1A-4A	PSIU1		
PSF12	CLOSE	OPEN	2:1	ON	(((A*B)+C)*D)*E)*F)				CHR1B	CHR2B	CHR3B	CHR4B	CHR51	CHR52	CHR53	CHR54	0	0	Water Flow Interlocks: PS1B-4B	PSIU2		
PSF13	CLOSE	OPEN	2	ON	(((A*B)+C)*D)*E)*F)				MAG5A	MAG6A	MAG5B	MAG5B	MAG51	MAG52	MAG53	MAG54	0	0	Water Flow Interlocks: PS5 & 6	PSIU3		
PSF14	CLOSE	OPEN	2	ON	(((A*B)+C)*D)*E)*F)				MAG7A	MAG8A	MAG7B	MAG8B	MAG51	MAG52	MAG53	MAG54	0	0	Water Flow Interlocks: PS7 & 8	PSIU4		
PSF15	CLOSE	OPEN	2:1	ON	(((A*B)+C)*D)*E)*F)				CAR9A	CAR10A	CAR11A	CAR12A	CAR51	CAR52	CAR53	CAR54	0	0	Water Flow Interlocks: PS9A-12A	PSIU5		
PSF16	CLOSE	OPEN	2	ON	(((A*B)+C)*D)*E)*F)				CAR9B	CAR10B	CAR11B	CAR12B	CAR51	CAR52	CAR53	CAR54	0	0	Water Flow Interlocks: PS9B-12B	PSIU6		
PSX11	CLOSE	OPEN	2	ON	(A*B)				CC5	CC6	CC6	CC6	CC6	CC6	CC6	CC6	0	0	Cover Interlocks - Chrome	PSIX1		
PSX12	CLOSE	OPEN	2:1	ON	(A*B)				CC5	CC6	CC6	CC6	CC6	CC6	CC6	CC6	0	0	Cover Interlocks - Chrome	PSIX2		
PSX13	CLOSE	OPEN	2	ON	(A*B)				CC9	CC10	CC10	CC10	CC10	CC10	CC10	CC10	0	0	Cover Interlocks - Mag	PSIX3		
PSX14	CLOSE	OPEN	2:1	ON	(A*B)				CC9	CC10	CC10	CC10	CC10	CC10	CC10	CC10	0	0	Cover Interlocks - Mag	PSIX4		
PSX15	CLOSE	OPEN	2	ON	(A*B)				CC11	CC12	CC12	CC12	CC12	CC12	CC12	CC12	0	0	Cover Interlocks - Carbon	PSIX5		
PSX16	CLOSE	OPEN	2:1	ON	(A*B)				CC11	CC12	CC12	CC12	CC12	CC12	CC12	CC12	0	0	Cover Interlocks - Carbon	PSIX6		
14	14	14	14	14	14	14	14	14	14	14	14	14	14	14	14	14	14	14	14	14		

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PG--PROGRAM BLOCK

3/07/91

TAG AD_ AP ST_SCA IS_IN IA_I DESC

PROGRAM

COMPG TH L 1 ON AUTO AB/Fix Communications Detect

00	MAXWAIT	10	
01	OPEN	CONTIN	
02	WAITFOR	CONTIN	= CLOSE
03	CLOSE	CONTIN	
04	NUL		
05	NUL		
06	NUL		
07	NUL		
08	NUL		
09	NUL		
10	NUL		
11	NUL		
12	NUL		
13	NUL		
14	NUL		
15	NUL		
16	NUL		
17	NUL		
18	NUL		
19	NUL		

CTRSTPG TH L 5 ON AUTO Pallet counter reset program

00	MAXWAIT	6	
01	IF	CTRST	= OPEN GOTO 4
02	WAITFOR	CTRST	= OPEN
03	OPEN	CTRST	
04	GOTO	0	
05	NUL		
06	NUL		
07	NUL		
08	NUL		
09	NUL		
10	NUL		
11	NUL		
12	NUL		
13	NUL		
14	NUL		
15	NUL		
16	NUL		
17	NUL		
18	NUL		
19	NUL		

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TAG

AD_ AP ST_SCA IS_IN IA_I DESC

PROGRAM

GASPG1 TH L 2:1 OFF AUTO Gas Control Heater 1

```

00 SETLIM      10.00
01 IF          GF1      = OPEN  GOTO 5
02 NUL
03 SETOUT      FLOST1    FLOSP1
04 GOTO        6
05 SETOUT      FLOST1    0
06 IF          GF2      = OPEN  GOTO 10
07 NUL
08 SETOUT      FLOST2    FLOSP2
09 GOTO        0
10 SETOUT      FLOST2    0
11 GOTO        0
12 NUL
13 NUL
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

GASPG2 TH L 2 OFF AUTO Gas Control Chrome

```

00 SETLIM      10.00
01 IF          GF3      = OPEN  GOTO 5
02 NUL
03 SETOUT      FLOST3    FLOSP3
04 GOTO        6
05 SETOUT      FLOST3    0
06 IF          GF4      = OPEN  GOTO 10
07 NUL
08 SETOUT      FLOST4    FLOSP4
09 GOTO        0
10 SETOUT      FLOSP4    0
11 GOTO        0
12 NUL
13 NUL
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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3/07/91

TAG AD AP ST SCA IS IN IA I DESC

PROGRAM

GASPG3 TH L 2:1 OFF AUTO Gas Control Mag

```

00 SETLIM      10.00
01 IF          GF5      = OPEN  GOTO 5
02 NUL
03 SETOUT      FLOST5    FLOSP5
04 GOTO        6
05 SETOUT      FLOST5    0
06 IF          GF6      = OPEN  GOTO 10
07 NUL
08 SETOUT      FLOST6    FLOSP6
09 GOTO        0
10 SETOUT      FLOST6    0
11 GOTO        0
12 NUL
13 NUL
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

GASPG4 TH L 2 OFF AUTO Gas Control Carbon

```

00 SETLIM      10.00
01 IF          GF7      = OPEN  GOTO 5
02 NUL
03 SETOUT      FLOST7    FLOSP7
04 GOTO        6
05 SETOUT      FLOST7    0
06 IF          GF8      = OPEN  GOTO 10
07 NUL
08 SETOUT      FLOST8    FLOSP8
09 GOTO        0
10 SETOUT      FLOSP8    0
11 GOTO        0
12 NUL
13 NUL
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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3/07/91

TAG AD_ AP ST_SCA IS_IN IA_I DESC

HTALPG TH L 2 ON AUTO Heater Alarm Program

PROGRAM

```

00 SETLIN 2.00
01 MAXWAIT 20
02 IF RH1A = OFF GOTO 6
03 WAITFOR RH1A = OFF
04 IF HVO1 < 10.0 GOTO 18
05 IF HVO2 < 10.0 GOTO 18
06 IF RH2A = OFF GOTO 11
07 WAITFOR RH2A = OFF
08 IF HVO3 < 10.0 GOTO 18
09 IF HVO4 < 10.0 GOTO 18
10 IF HVO5 < 10.0 GOTO 18
11 IF RH3A = OFF GOTO 16
12 WAITFOR RH3A = OFF
13 IF HVO6 < 10.0 GOTO 18
14 IF HVO7 < 10.0 GOTO 18
15 IF HVO8 < 10.0 GOTO 18
16 OPEN HTALM
17 GOTO 0
18 CLOSE HTALM
19 GOTO 0

```

PGRUN TH L 30 ON AUTO Run Flow and Pressure Blocks

```

00 IF AUTO1 != Off GOTO 9
01 IF AUTO2 != Off GOTO 9
02 STOP CH2
03 STOP CH3
04 STOP CH4
05 STOP FLO3
06 STOP FLO5
07 STOP FLO7
08 GOTO 0
09 RUN CH2
10 RUN CH3
11 RUN CH4
12 RUN FLO3
13 RUN FLO5
14 RUN FLO7
15 GOTO 0
16 NUL
17 NUL
18 NUL
19 NUL

```

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3/07/91

TAG	AD	AP	ST_SCA	IS_IN	IA_I	DESC	PROGRAM
PSALPG1	TH	L	3	ON		AUTO Power Supply Setpoint Alarm	<pre> 00 MAXWAIT 20 01 NUL 02 IF PSOM1 = Off GOTO 6 03 WAITFOR PSSR1A = OPEN 04 IF PSSR1A = CLOSE GOTO 12 05 IF PSSR1B = CLOSE GOTO 12 06 IF PSOM2 = Off GOTO 10 07 WAITFOR PSSR2A = OPEN 08 IF PSSR2A = CLOSE GOTO 12 09 IF PSSR2B = CLOSE GOTO 12 10 OPEN CHRAL1 11 GOTO 0 12 CLOSE CHRAL1 13 GOTO 0 14 NUL 15 NUL 16 NUL 17 NUL 18 NUL 19 NUL </pre>
PSALPG10	TH	L	3	ON		AUTO Power Supply Setpoint Alarm	<pre> 00 MAXWAIT 20 01 NUL 02 IF PSOM3 = Off GOTO 6 03 WAITFOR PSARC3A = OPEN 04 IF PSARC3A = OPEN GOTO 12 05 IF PSARC3B = OPEN GOTO 12 06 IF PSOM4 = Off GOTO 10 07 WAITFOR PSARC4A = OPEN 08 IF PSARC4A = OPEN GOTO 12 09 IF PSARC4B = OPEN GOTO 12 10 OPEN CHARC2 11 GOTO 0 12 CLOSE CHARC2 13 GOTO 0 14 NUL 15 NUL 16 NUL 17 NUL 18 NUL 19 NUL </pre>

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TAG AD AP ST_SCA IS_IN IA_I DESC

PROGRAM

PSALPG11 TH L 3:1 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PS0N7 = Off GOTO 6
03 WAITFOR PSARC7A = OPEN
04 IF PSARC7A = OPEN GOTO 12
05 IF PSARC7B = OPEN GOTO 12
06 IF PS0N8 = Off GOTO 10
07 WAITFOR PSARC8A = OPEN
08 IF PSARC8A = OPEN GOTO 12
09 IF PSARC8B = OPEN GOTO 12
10 OPEN MGARC2
11 GOTO 0
12 CLOSE MGARC2
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

PSALPG12 TH L 3:2 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PS0N11 = Off GOTO 6
03 WAITFOR PSARC11A = OPEN
04 IF PSARC11A = OPEN GOTO 12
05 IF PSARC11B = OPEN GOTO 12
06 IF PS0N12 = Off GOTO 10
07 WAITFOR PSARC20 = OPEN
08 IF PSARC20 = OPEN GOTO 12
09 NUL
10 OPEN CAARC2
11 GOTO 0
12 CLOSE CAARC2
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```


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3/07/91

TAG AD AP ST_SCA IS_IN IA_I DESC

PROGRAM

PSALPG2 TH L 3:1 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSOW5 = Off GOTO 6
03 WAITFOR PSSR5A = OPEN
04 IF PSSR5A = CLOSE GOTO 12
05 IF PSSR5B = CLOSE GOTO 12
06 IF PSOW6 = Off GOTO 10
07 WAITFOR PSSR6A = OPEN
08 IF PSSR6A = CLOSE GOTO 12
09 IF PSSR6B = CLOSE GOTO 12
10 OPEN MAGAL1
11 GOTO 0
12 CLOSE MAGAL1
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

PSALPG3 TH L 3:2 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSOW9 = Off GOTO 6
03 WAITFOR PSSR9A = OPEN
04 IF PSSR9A = CLOSE GOTO 12
05 IF PSSR9B = CLOSE GOTO 12
06 IF PSOW10 = Off GOTO 10
07 WAITFOR PSSR10A = OPEN
08 IF PSSR10A = CLOSE GOTO 12
09 IF PSSR10B = CLOSE GOTO 12
10 OPEN CARAL1
11 GOTO 0
12 CLOSE CARAL1
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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TAG

AD_ AP ST_SCA IS_IN IA_I DESC

PROGRAM

PSALPG4 TH L 3 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSON3 = Off GOTO 6
03 WAITFOR PSSR3A = OPEN
04 IF PSSR3A = CLOSE GOTO 12
05 IF PSSR3B = CLOSE GOTO 12
06 IF PSON4 = Off GOTO 10
07 WAITFOR PSSR4A = OPEN
08 IF PSSR4A = CLOSE GOTO 12
09 IF PSSR4B = CLOSE GOTO 12
10 OPEN CHRAL2
11 GOTO 0
12 CLOSE CHRAL2
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

PSALPG5 TH L 3:1 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSON7 = Off GOTO 6
03 WAITFOR PSSR7A = OPEN
04 IF PSSR7A = CLOSE GOTO 12
05 IF PSSR7B = CLOSE GOTO 12
06 IF PSON8 = Off GOTO 10
07 WAITFOR PSSR8A = OPEN
08 IF PSSR8A = CLOSE GOTO 12
09 IF PSSR8B = CLOSE GOTO 12
10 OPEN MAGAL2
11 GOTO 0
12 CLOSE MAGAL2
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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TAG AD AP ST_SCA IS_IN IA_1 DESC

PROGRAM

PSALPG6 TH L 3:2 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSON11 = Off GOTO 6
03 WAITFOR PSSR11A = OPEN
04 IF PSSR11A = CLOSE GOTO 12
05 IF PSSR11B = CLOSE GOTO 12
06 IF PSON12 = Off GOTO 10
07 WAITFOR PSSR12A = OPEN
08 IF PSSR12A = CLOSE GOTO 12
09 IF PSSR12B = CLOSE GOTO 12
10 OPEN CARAL2
11 GOTO 0
12 CLOSE CARAL2
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

PSALPG7 TH L 3 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSON1 = Off GOTO 6
03 WAITFOR PSARC1A = OPEN
04 IF PSARC1A = OPEN GOTO 12
05 IF PSARC1B = OPEN GOTO 12
06 IF PSON2 = Off GOTO 10
07 WAITFOR PSARC2A = OPEN
08 IF PSARC2A = OPEN GOTO 12
09 IF PSARC2B = OPEN GOTO 12
10 OPEN CHARC1
11 GOTO 0
12 CLOSE CHARC1
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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3/07/91

TAG AD_ AP ST_SCA IS_IN IA_I DESC

PROGRAM

PSALPG8 TH L 3:1 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSON5 = Off GOTO 6
03 WAITFOR PSARC5A = OPEN
04 IF PSARC5A = OPEN GOTO 12
05 IF PSARC5B = OPEN GOTO 12
06 IF PSON6 = Off GOTO 10
07 WAITFOR PSARC6A = OPEN
08 IF PSARC6A = OPEN GOTO 12
09 IF PSARC6B = OPEN GOTO 12
10 OPEN MGARC1
11 GOTO 0
12 CLOSE MGARC1
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

PSALPG9 TH L 3:2 ON AUTO Power Supply Setpoint Alarm

```

00 MAXWAIT 20
01 NUL
02 IF PSON9 = Off GOTO 6
03 WAITFOR PSARC9A = OPEN
04 IF PSARC9A = OPEN GOTO 12
05 NUL
06 IF PSON10 = Off GOTO 10
07 WAITFOR PSARC10A = OPEN
08 IF PSARC10A = OPEN GOTO 12
09 IF PSARC10B = OPEN GOTO 12
10 OPEN CAARC1
11 GOTO 0
12 CLOSE CAARC1
13 GOTO 0
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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TAG AD AP ST_SCA IS_IN IA_I DESC

PROGRAM

PSFPG1 TH L 6 ON AUTO Change PFS Value

```

00 1  != Off  GOTO 3
01 SETOUT PSF1      1
02 GOTO 4
03 SETOUT PSF1      2
04 2  != Off  GOTO 7
05 SETOUT PSF2      1
06 GOTO 8
07 SETOUT PSF2      2
08 3  != Off  GOTO 11
09 SETOUT PSF3      1
10 GOTO 12
11 SETOUT PSF3      2
12 4  != Off  GOTO 15
13 SETOUT PSF4      1
14 GOTO 0
15 SETOUT PSF4      2
16 GOTO 0
17 NUL
18 NUL
19 NUL

```

PSFPG2 TH L 6:2 ON AUTO Change PFS Value

```

00 5  != Off  GOTO 3
01 SETOUT PSF5      1
02 GOTO 4
03 SETOUT PSF5      2
04 6  != Off  GOTO 7
05 SETOUT PSF6      1
06 GOTO 8
07 SETOUT PSF6      2
08 7  != Off  GOTO 11
09 SETOUT PSF7      1
10 GOTO 12
11 SETOUT PSF7      2
12 8  != Off  GOTO 15
13 SETOUT PSF8      1
14 GOTO 0
15 SETOUT PSF8      2
16 GOTO 0
17 NUL
18 NUL
19 NUL

```

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TAG AD AP ST_SCA IS_IN IA_I DESC

PSFPG3 TH L 6:4 ON AUTO Change PFS Value

PROGRAM

```

00 9  != Off  GOTO 3
01 SETOUT PSF9      1
02 GOTO 4
03 SETOUT PSF9      2
04 10 != Off  GOTO 7
05 SETOUT PSF10     1
06 GOTO 8
07 SETOUT PSF10     2
08 11 != Off  GOTO 11
09 SETOUT PSF11     1
10 GOTO 12
11 SETOUT PSF11     2
12 12 != Off  GOTO 15
13 SETOUT PSF12     1
14 GOTO 0
15 SETOUT PSF12     2
16 GOTO 0
17 NUL
18 NUL
19 NUL

```

PSV11 TH L 3 ON AUTO Power Supply Vacuum Interlock - Chrome

```

00 IF TC6 = OPEN GOTO 5
01 IF PSIV1 = CLOSE GOTO 0
02 CLOSE PSIV1
03 CLOSE PSIV2
04 GOTO 0
05 IF PSIV1 = OPEN GOTO 0
06 OPEN PSIV1
07 OPEN PSIV2
08 GOTO 0
09 NUL
10 NUL
11 NUL
12 NUL
13 NUL
14 NUL
15 NUL
16 NUL
17 NUL
18 NUL
19 NUL

```

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TAG	AD	AP	ST	SCA	IS	IN	IA	I	DESC	PROGRAM
PSV12	TH	L	3:1	ON					AUTO Power Supply Vacuum Interlock - Mag	00 IF TC11 = OPEN GOTO 5 01 IF PSIV3 = CLOSE GOTO 0 02 CLOSE PSIV3 03 CLOSE PSIV4 04 GOTO 0 05 IF PSIV3 = OPEN GOTO 0 06 OPEN PSIV3 07 OPEN PSIV4 08 GOTO 0 09 NUL 10 NUL 11 NUL 12 NUL 13 NUL 14 NUL 15 NUL 16 NUL 17 NUL 18 NUL 19 NUL
PSV13	TH	L	3:2	ON					AUTO Power Supply Vacuum Interlock - Carbon	00 IF TC16 = OPEN GOTO 5 01 IF PSIV5 = CLOSE GOTO 0 02 CLOSE PSIV5 03 CLOSE PSIV6 04 GOTO 0 05 IF PSIV5 = OPEN GOTO 0 06 OPEN PSIV5 07 OPEN PSIV6 08 GOTO 0 09 NUL 10 NUL 11 NUL 12 NUL 13 NUL 14 NUL 15 NUL 16 NUL 17 NUL 18 NUL 19 NUL

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3/07/91						PROGRAM
TAG	AD_	AP	ST_SCA	IS_IN	IA_I	DESC
RCPPG	TH	L	3	ON		AUTO Select Recipe to Load
00	IF					SELRCP1 != CLOSE GOTO 2
01	SETOUT					RCPREG 1
02	IF					SELRCP2 != CLOSE GOTO 4
03	SETOUT					RCPREG 2
04	IF					SELRCP3 != CLOSE GOTO 6
05	SETOUT					RCPREG 3
06	IF					SELRCP4 != CLOSE GOTO 0
07	SETOUT					RCPREG 4
08	GOTO					0
09	NUL					
10	NUL					
11	NUL					
12	NUL					
13	NUL					
14	NUL					
15	NUL					
16	NUL					
17	NUL					
18	NUL					
19	NUL					
TD1PROG	TH	L	3:1	ON		AUTO Cryo #1 Temperature Select
00	IF					TD1 <= 2.22 GOTO 4
01	SETOUT					85
02	SETOUT					63
03	GOTO					6
04	SETOUT					58
05	SETOUT					00
06	IF					TD2 <= 2.22 GOTO 10
07	SETOUT					85
08	SETOUT					63
09	GOTO					12
10	SETOUT					58
11	SETOUT					00
12	IF					TD3 <= 2.22 GOTO 16
13	SETOUT					85
14	SETOUT					63
15	GOTO					0
16	SETOUT					58
17	SETOUT					00
18	GOTO					0
19	NUL					

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3/07/91

TAG	AD	AP	ST	SCA	IS	IN	IA	I	DESC	PROGRAM
TD2PROG	TH	L	3:2	ON					AUTO Cryo #1 Temperature Select	00 IF TD4 <= 2.22 GOTO 4 01 SETOUT 85 02 SETOUT 63 03 GOTO 6 04 SETOUT 58 05 SETOUT 00 06 IF TD5 <= 2.22 GOTO 10 07 SETOUT 85 08 SETOUT 63 09 GOTO 12 10 SETOUT 58 11 SETOUT 00 12 IF TD6 <= 2.22 GOTO 16 13 SETOUT 85 14 SETOUT 63 15 GOTO 0 16 SETOUT 58 17 SETOUT 00 18 GOTO 0 19 MUL
TD3PROG	TH	L	3	ON					AUTO Cryo 3 Temperature Select	00 IF TD7 <= 2.22 GOTO 4 01 SETOUT 85 02 SETOUT 63 03 GOTO 6 04 SETOUT 58 05 SETOUT 00 06 IF TD8 <= 2.22 GOTO 10 07 SETOUT 85 08 SETOUT 63 09 GOTO 12 10 SETOUT 58 11 SETOUT 00 12 IF TD9 <= 2.22 GOTO 16 13 SETOUT 85 14 SETOUT 63 15 GOTO 0 16 SETOUT 58 17 SETOUT 00 18 GOTO 0 19 MUL

682

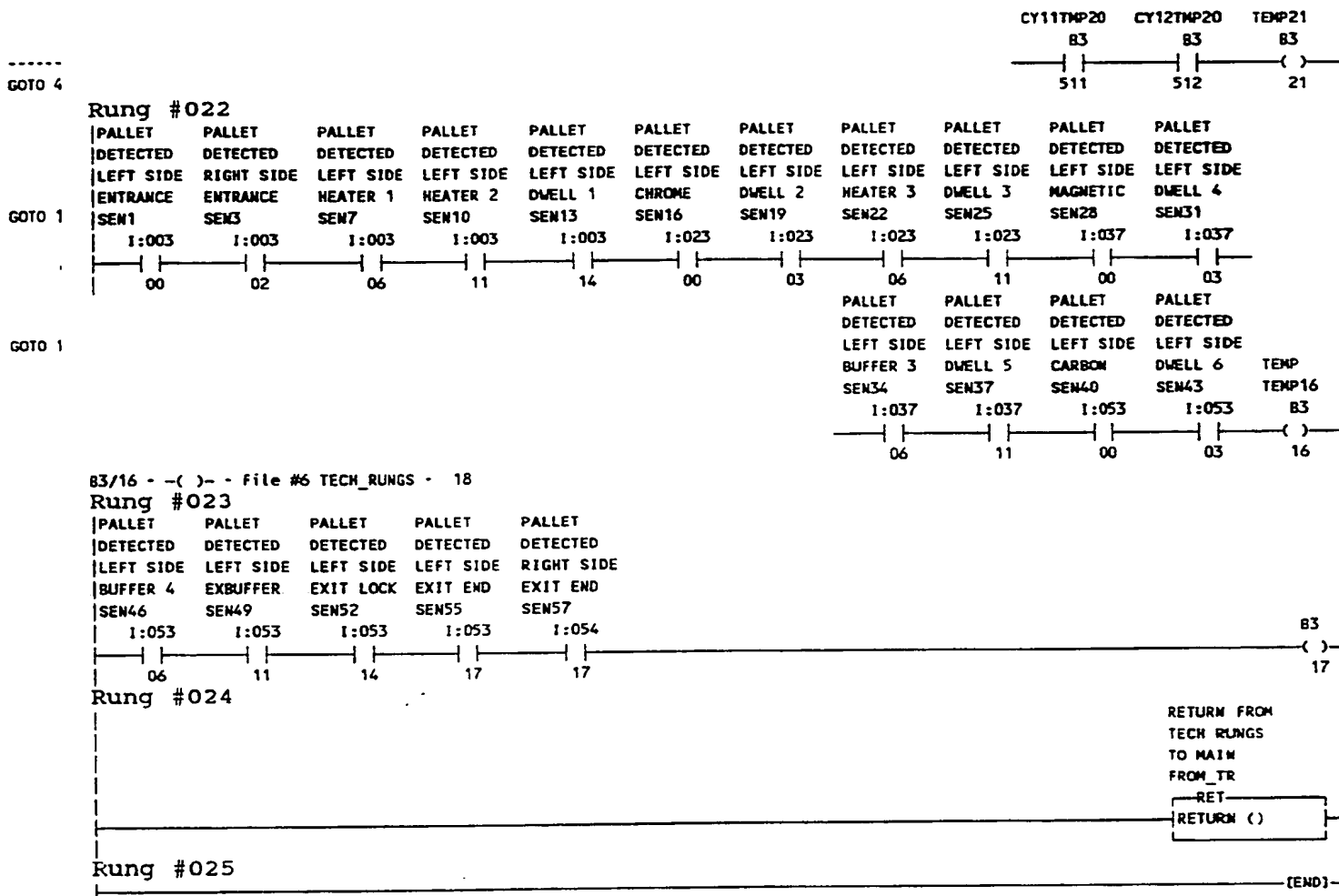
3/07/91

TAG	AD	AP	ST	SCA	IS	IN	IA	I	DESC
TD4PROG	TH	L	3:1	ON					AUTO Cryo 4 Temperature Select

PROGRAM

00	IF	TD10	<=	2.22	GOTO 4
01	SETOUT	85			
02	SETOUT	63			
03	GOTO	6			
04	SETOUT	58			
05	SETOUT	00			
06	IF	TD11	<=	2.22	GOTO 10
07	SETOUT	58			
08	SETOUT	63			
09	GOTO	12			
10	SETOUT	58			
11	SETOUT	00			
12	IF	TD12	<=	2.22	GOTO 16
13	SETOUT	85			
14	SETOUT	63			
15	GOTO	0			
16	SETOUT	58			
17	SETOUT	00			
18	GOTO	0			
19	NUL				

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The apparatus of the present invention provides a high-speed in-line sputtering apparatus for producing superior multilayer films on substrates, such as disks suitable for use in Winchester-type hard disk drives.

5 The process of the present invention provides an improved method of providing multilayer coatings to a variety of substrate types at a much greater rate than prior art methods.

Also described herein are a novel means for heating

10 substrates to be coated, a novel sputtering magnetron design, a novel, variable speed, overhead, non-contaminating substrate transportation system and a comprehensive, centralized, programmable electronic means for controlling the apparatus and process are

15 provided. Still further, when the process and apparatus are used for providing magnetic coatings for substrates, such as disks, to be utilized in hard disk drives using Winchester-type technology, a unique disk texturing method for improving the disk's magnetic recording

20 properties, and a novel disk carrier (or pallet) design which contributes to uniform substrate heating characteristics in a large, single, high capacity pallet, are also provided herein. Numerous variations are possible as will be apparent to those skilled in the

25 art; such variations are intended to be within the scope of the invention as defined by this specification and the following claims are intended to cover all the modifications and equivalents falling within the scope of the invention.

30

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CLAIMSWhat is claimed is:

- 5 1. A high throughput sputtering apparatus for providing a single or multi-layer coating to the surface of a plurality of substrates, said apparatus including a plurality of buffer and sputtering chambers, and an input end and an output end, wherein said substrates are transported through said chambers of said apparatus at
- 10 varying rates of speed such that the rate of speed of a pallet from said input end to said output end is a constant for each of said plurality of pallets.
- 15 2. A high throughput sputtering apparatus having a plurality of integrally matched components, said components comprising:
- 20 means for sputtering a multi-layer coating onto a plurality of substrates, said means for sputtering including a series of sputtering chambers each having relative isolation from adjacent chambers to reduce cross contamination between the coating components being sputtered onto substrates therein, said sputtering chambers being isolated from ambient atmospheric conditions;
- 25 means for transporting said plurality of substrates through said means for sputtering at variable velocities;
- 30 means for reducing the ambient pressure within said means for sputtering to a vacuum level within a pressure range sufficient to enable sputtering operation;
- means for heating said plurality of substrates to a temperature conducive to sputtering said multi-layer coatings thereon, said means for heating providing a

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substantially uniform temperature profile over the surface of said substrate; and

control means for providing control signals to, and for receiving feedback input from, said means for sputtering, means for transporting, means for reducing and means for heating, said control means being programmable for allowing control over said means for sputtering, means for transporting, means for reducing and means for heating.

10

3. A high throughput sputtering apparatus, comprising:

control means for providing control signals and for monitoring a plurality of sensory input signals;

15

means for transporting a plurality of substrates through a sequential series of concurrent sputtering steps at selected variable velocities responsive to said control signals, said means including a first set of means for providing said sensory input signals to said control means;

20

means for reducing the ambient pressure within the apparatus to a common reduced pressure level within a pressure range to enable sputtering operation responsive to said control means, said means for reducing including a second set of means for providing said sensory input signals to said control means;

25

means for heating said plurality of substrates to an ambient temperature, said temperature having a substantially uniform profile over the surface of said substrate, said means for heating including a third set of means for providing said sensory input signals to said control means;

30

and

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means for sputtering a multi-layer coating onto said substrate responsive to said control means, said means for sputtering including a third set of means for providing said sensory input signals to said control means.

4. A high throughput direct current magnetron sputtering process for producing multilayer thin films, comprising the steps of:
- 10 providing substrates to be sputtered;
 - creating an environment about said substrates, said environment having a pressure within a pressure range which would enable sputtering operations;
 - 15 providing a gas into said environment in a plasma state and within said pressure range to carry out sputtering operations;
 - transporting substrates at varying velocities through said environment a sequence of sputtering steps within said environment and along a return path external
 - 20 to said environment, and simultaneously introducing the substrates into said environment without substantially disrupting said pressure of said environment,
 - providing rapid and uniform heating of said
 - 25 substrates to optimize film integrity during sputtering steps, and
 - sputtering said substrates to provide successive layers of thin films on the substrates;
 - and
 - 30 removing the sputtered substrates without contaminating said environment.

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5. A high throughput direct current sputtering process for producing multilayer thin films on magnetic recording media, comprising the steps of:

providing substrates;

5 physically abrading the substrates to achieve a uniform texture of intersecting circumferential lines across the substrate surface;

cleaning said substrates;

10 providing a sputtering environment about said substrates, said environment having a pressure within a pressure range to enable sputtering operations;

15 loading the substrates into a high capacity carrier of sufficient dimensions to accommodate substrate and carrier thermal expansion and enhance thermal uniformity between individual substrates;

introducing the substrates into said environment without disrupting said environment;

20 transporting the substrates at varying velocities through said environment a return path external to said environment while protecting substrates from contamination;

providing a gas in a plasma state into said environment at a pressure sufficient to carry out sputtering operations;

25 providing rapid and uniform heating of the substrates to optimize film integrity during subsequent sputtering steps;

sputtering to provide successive layers of thin films on said substrates; and

30 removing the coated substrates without disrupting sputtering operations.

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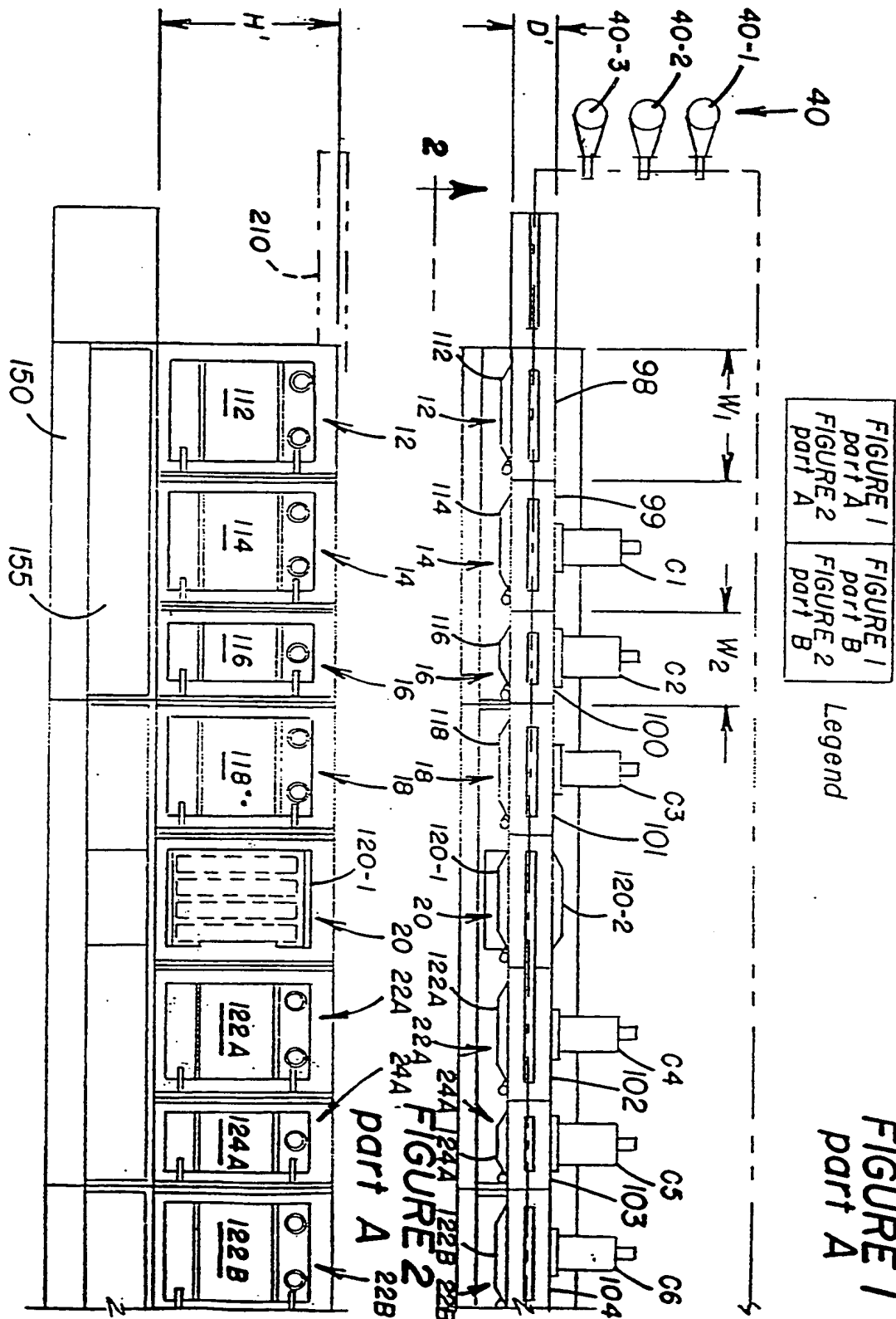
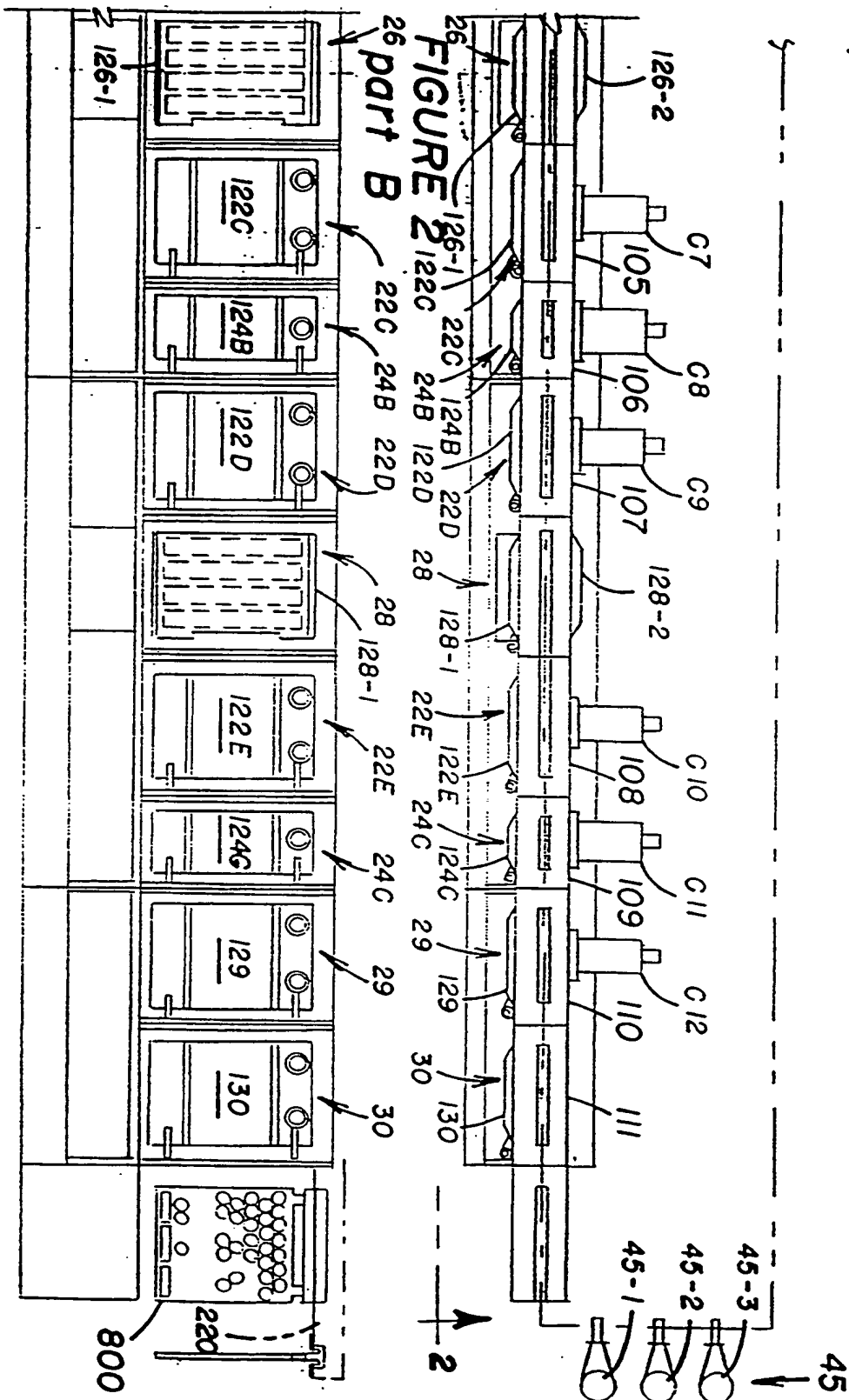
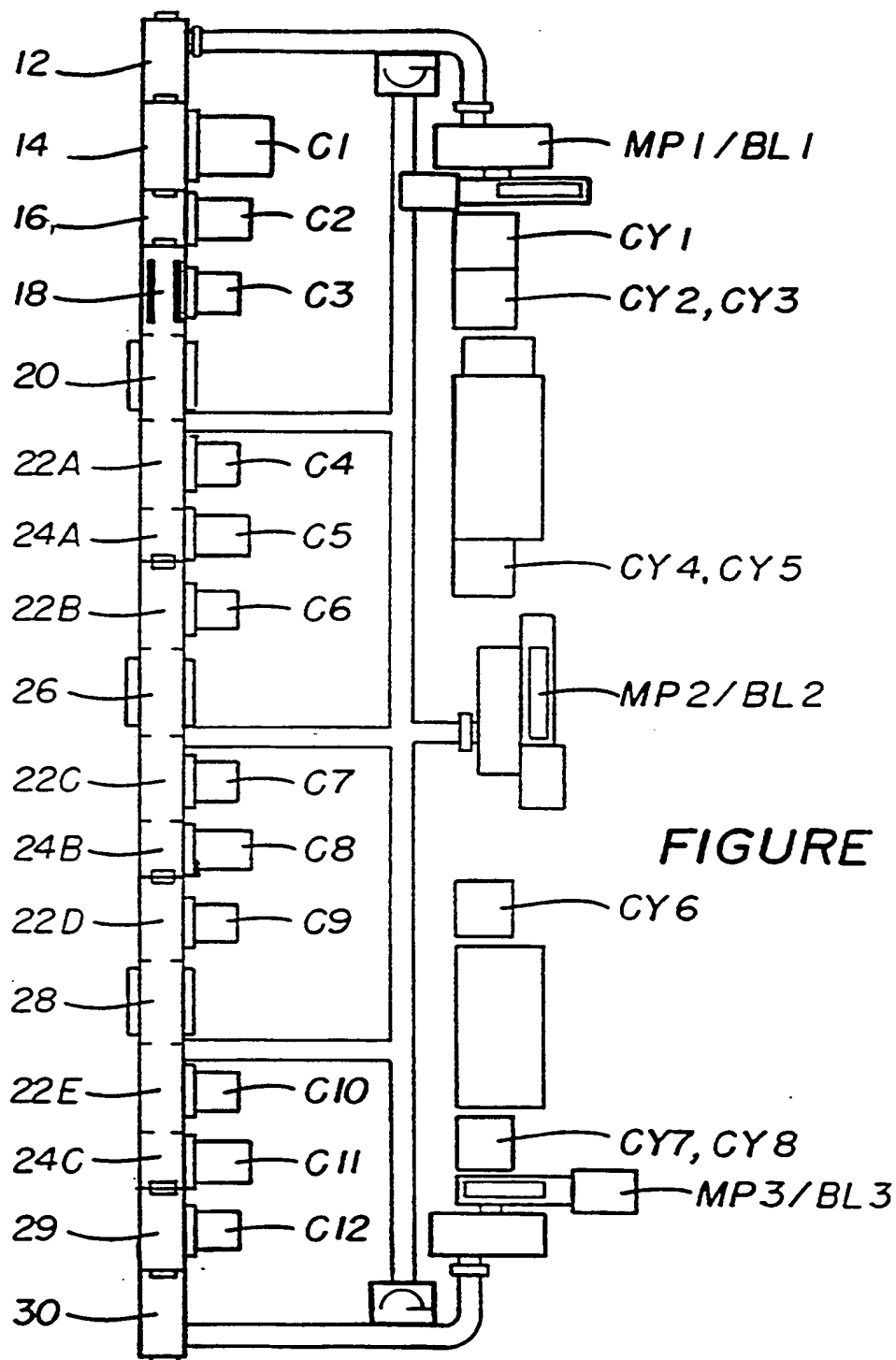
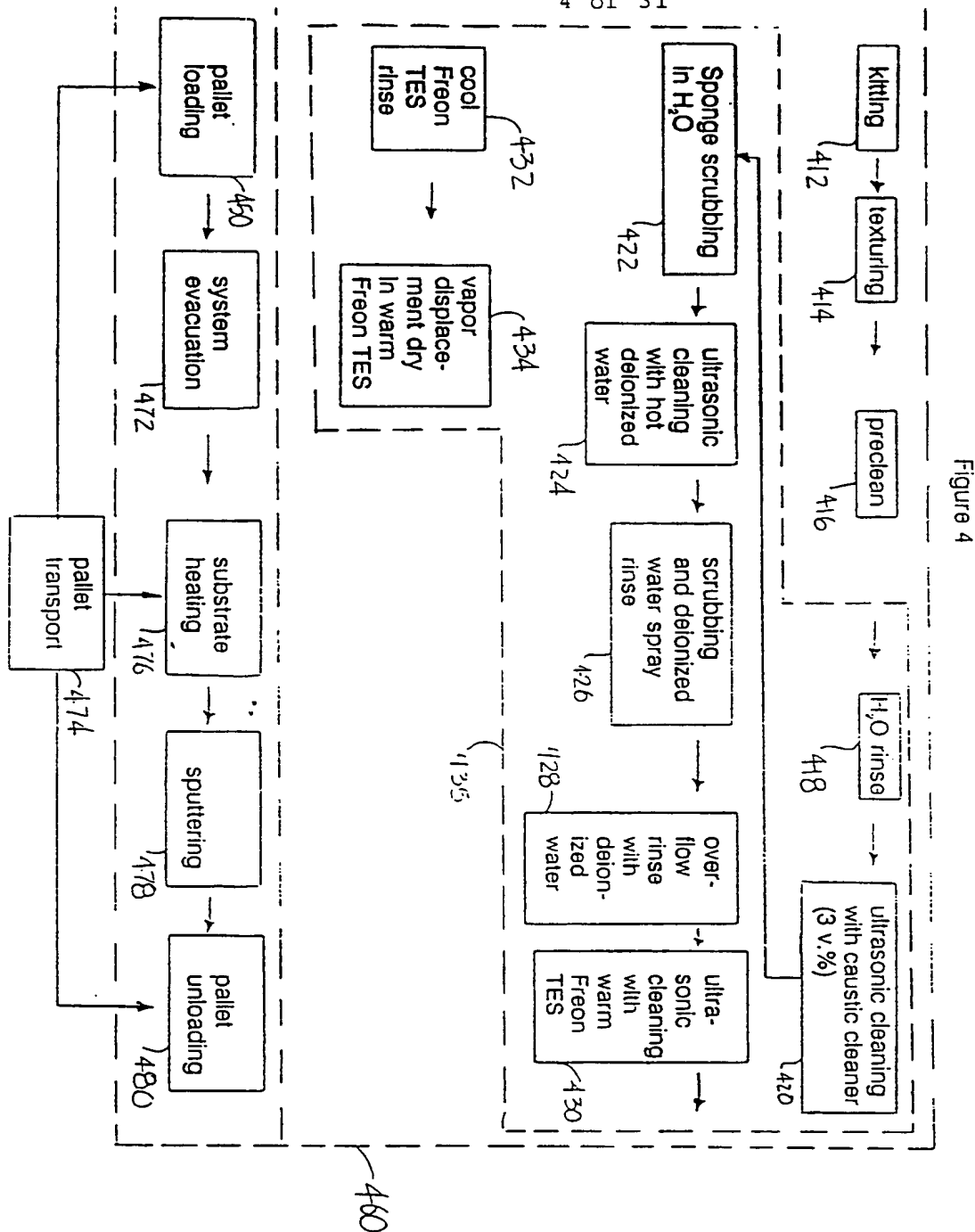


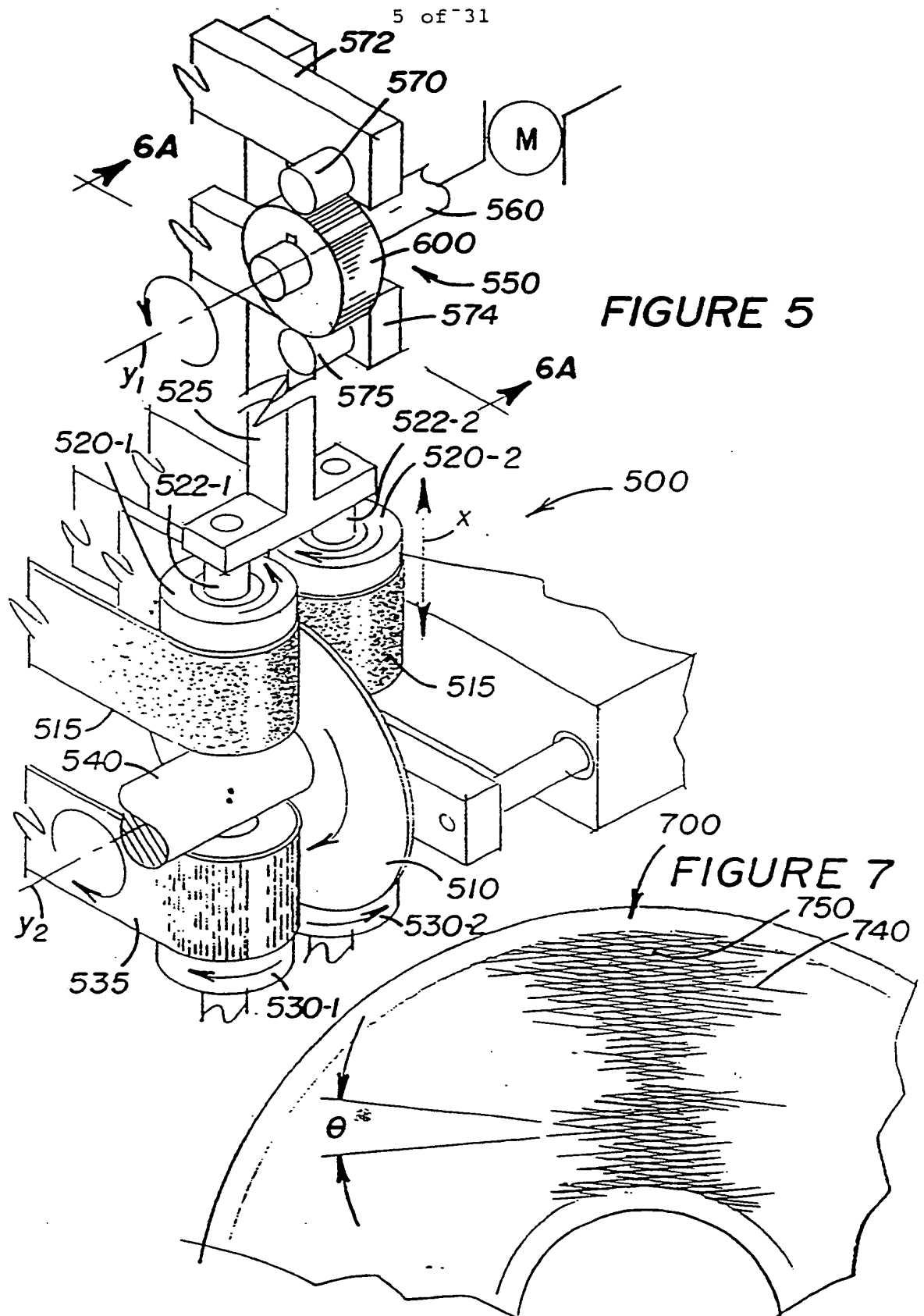
FIGURE 1
part B



**FIGURE 3**

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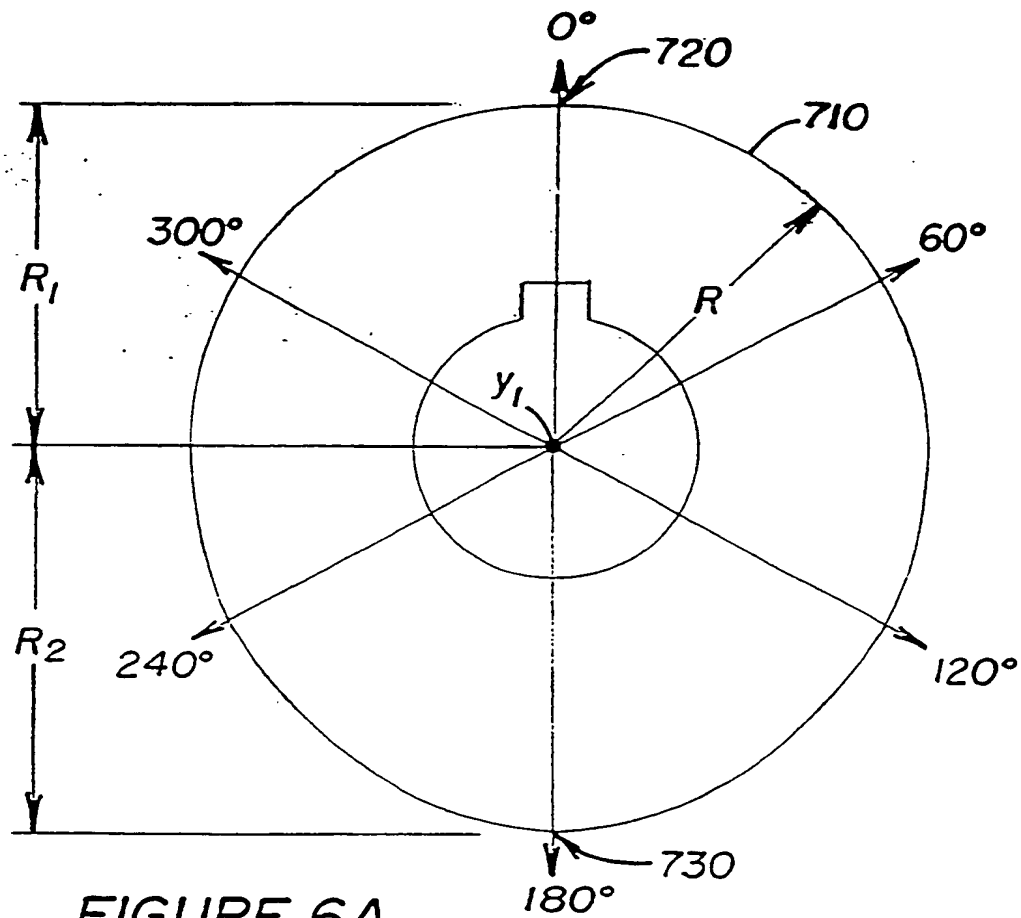


FIGURE 6A

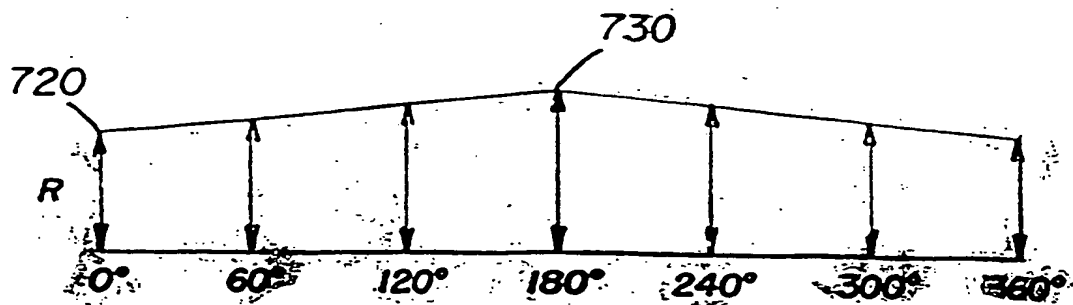


FIGURE 6B

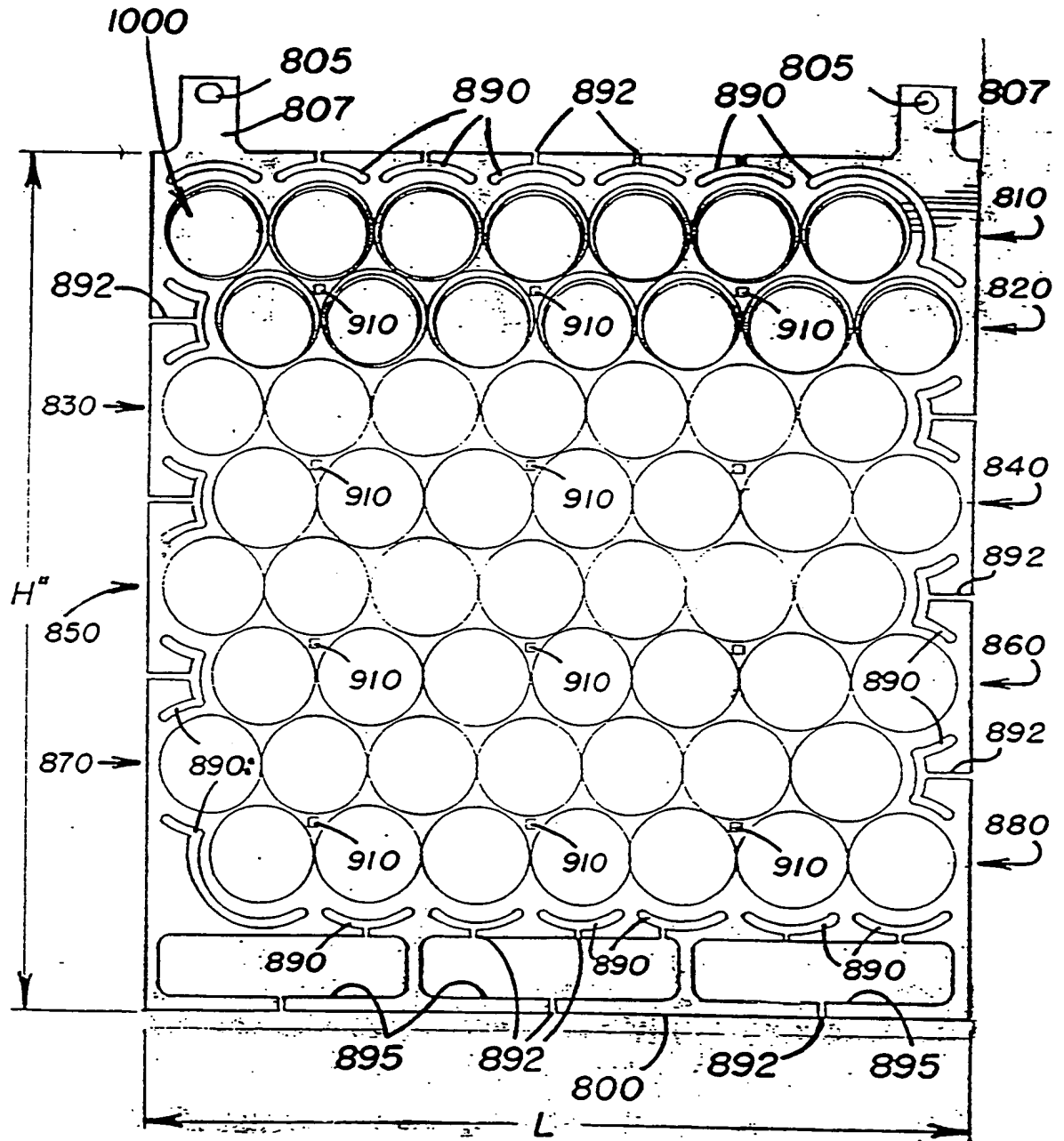
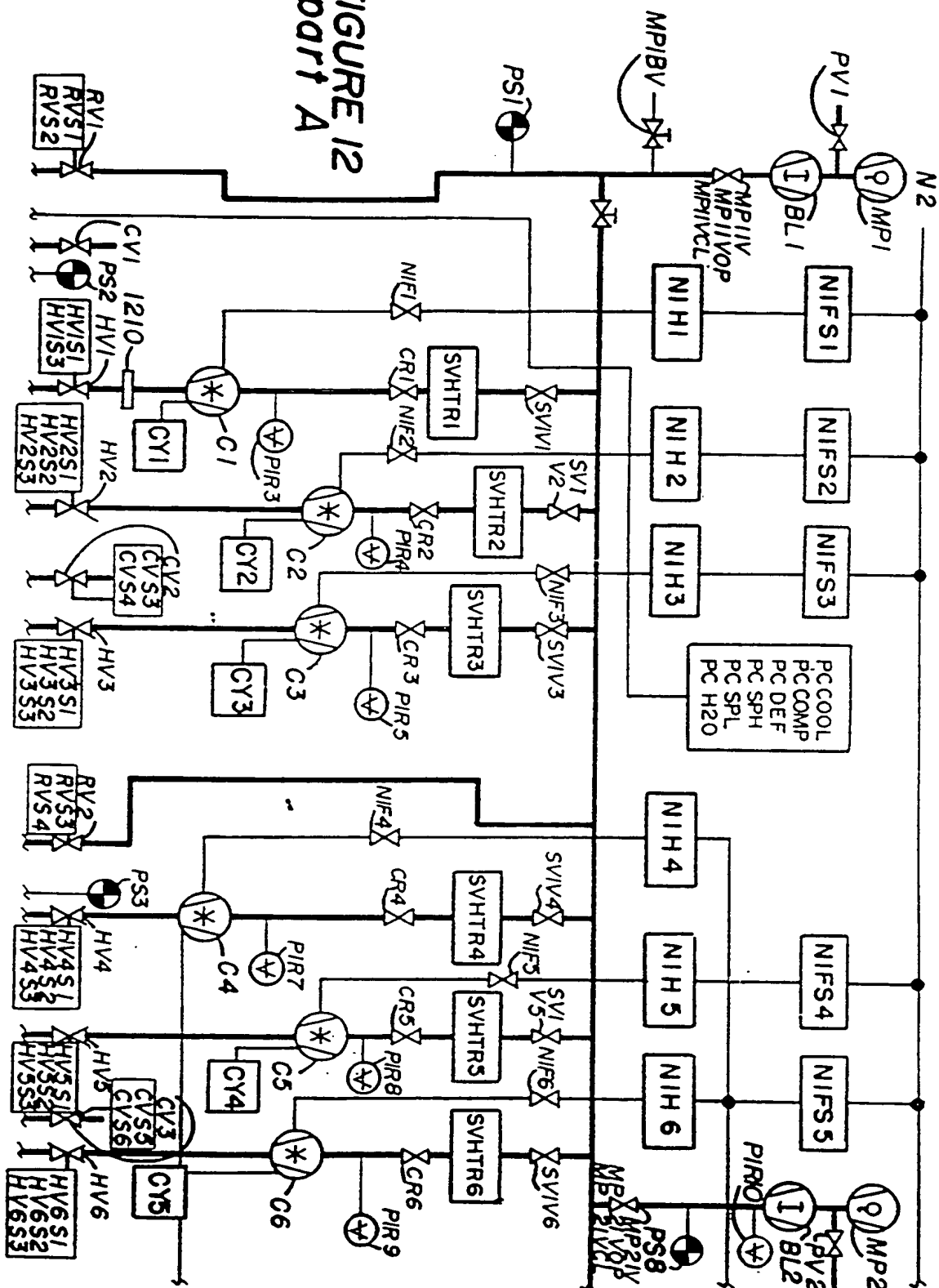
**FIGURE 8**

FIGURE 12
part A

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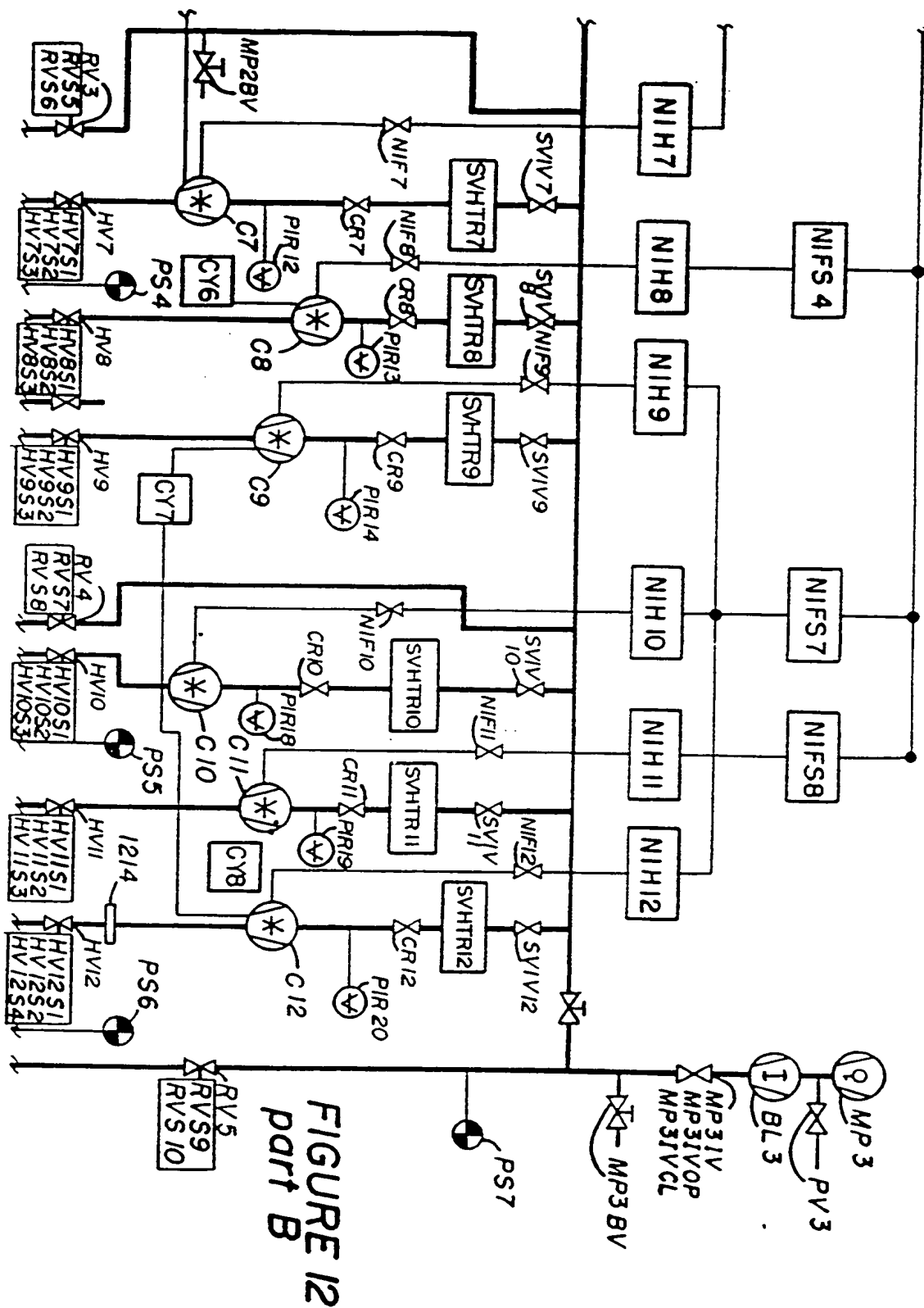
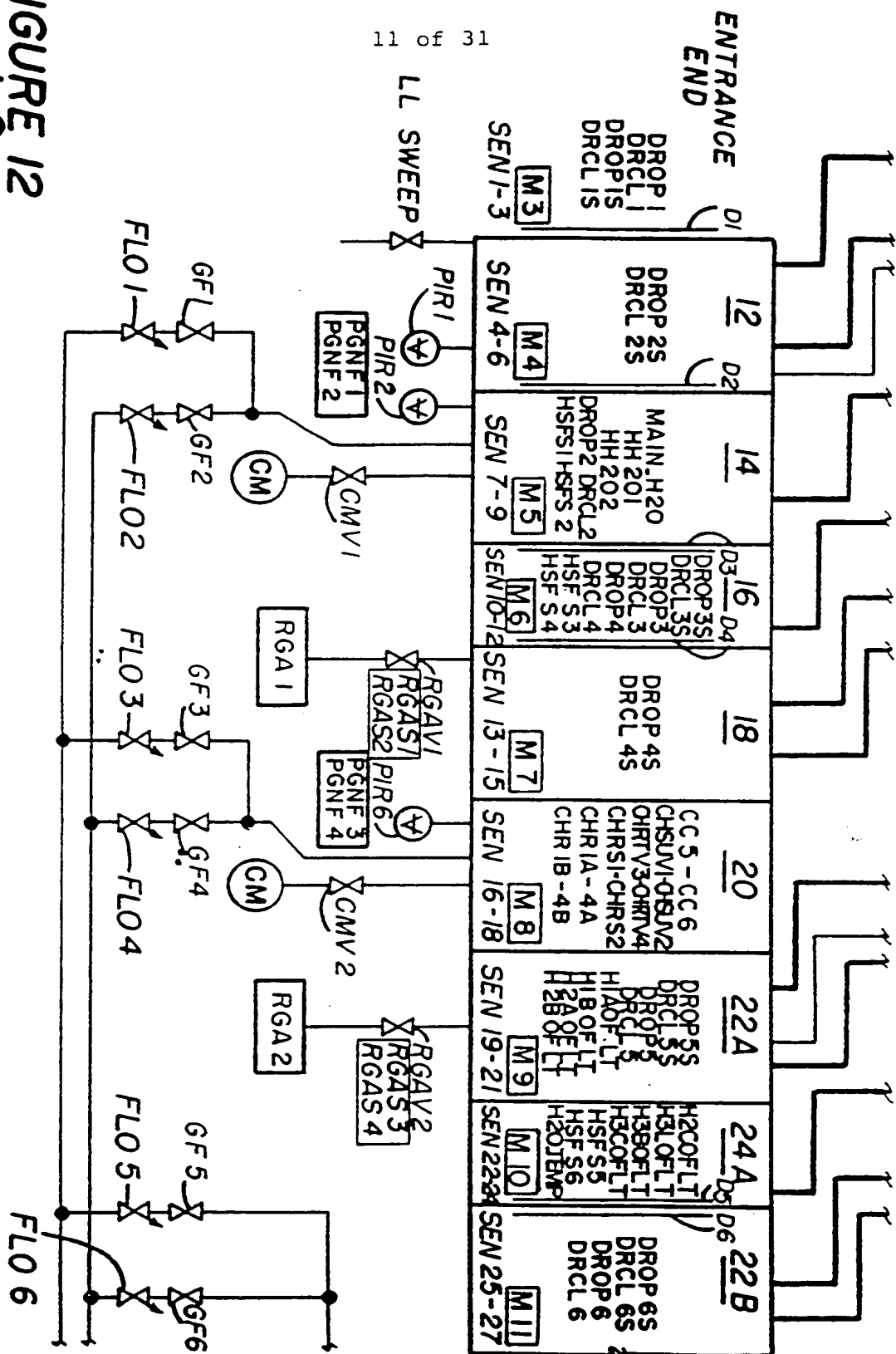


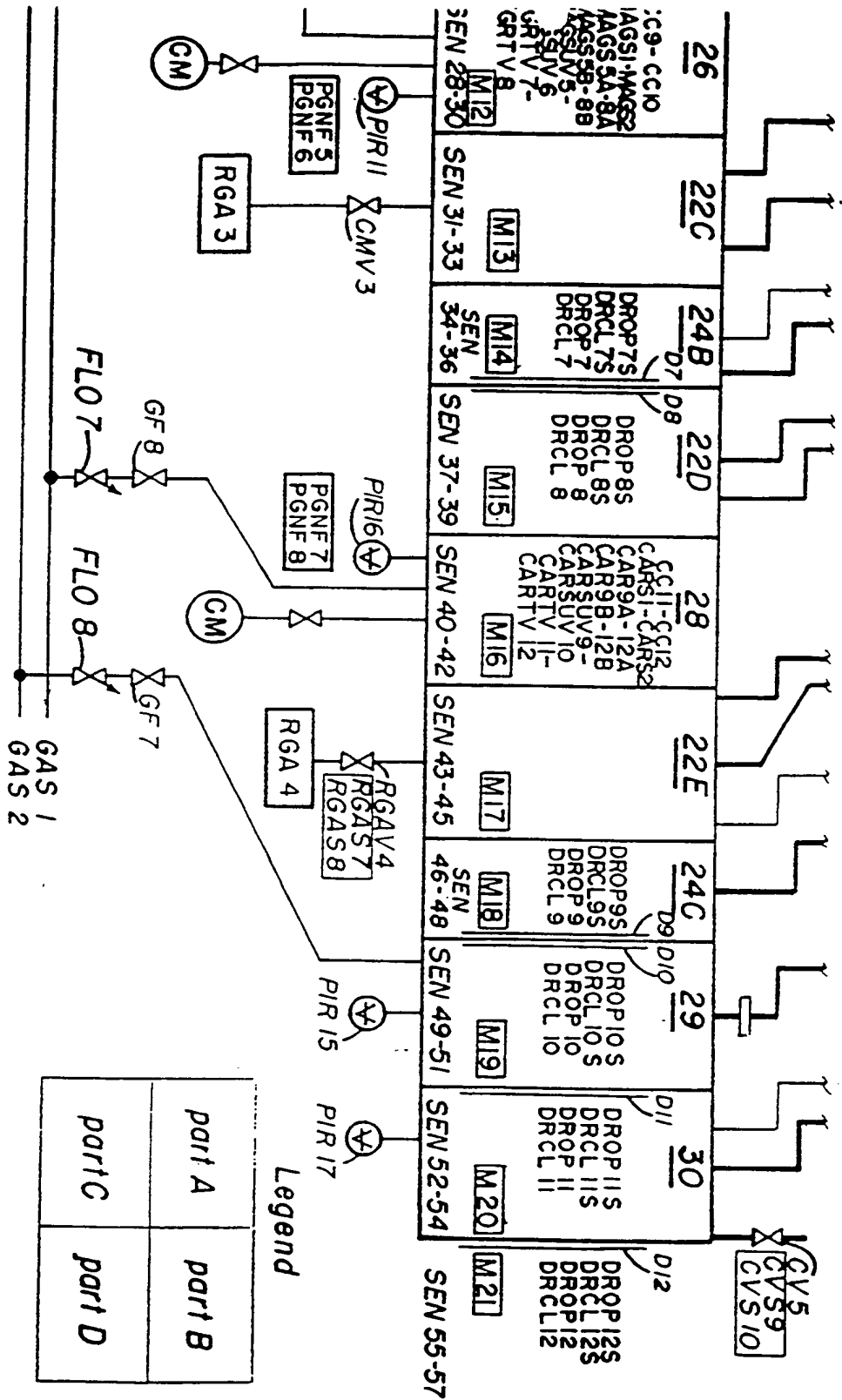
FIGURE 12
part B

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FIGURE 12
part C



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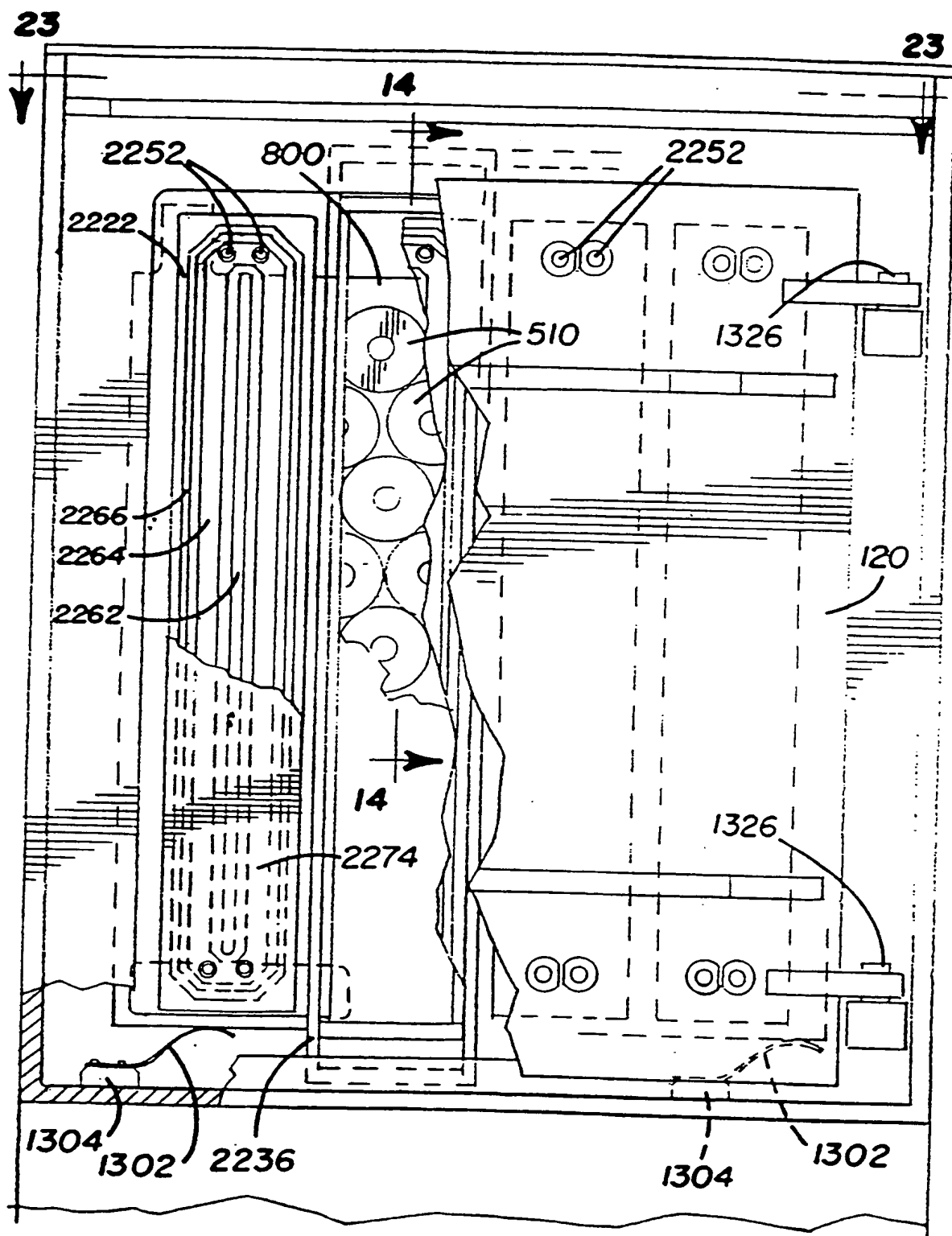
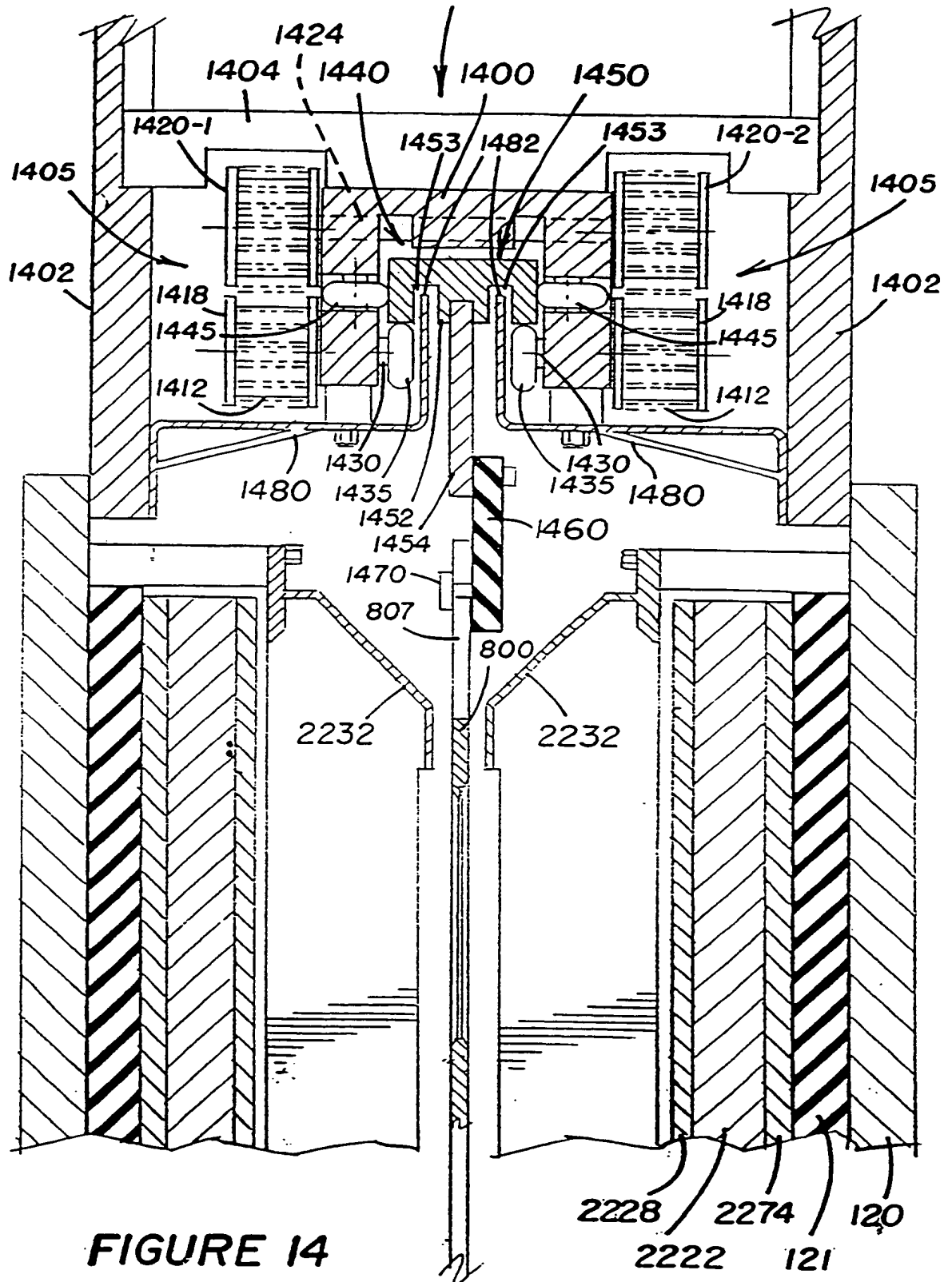


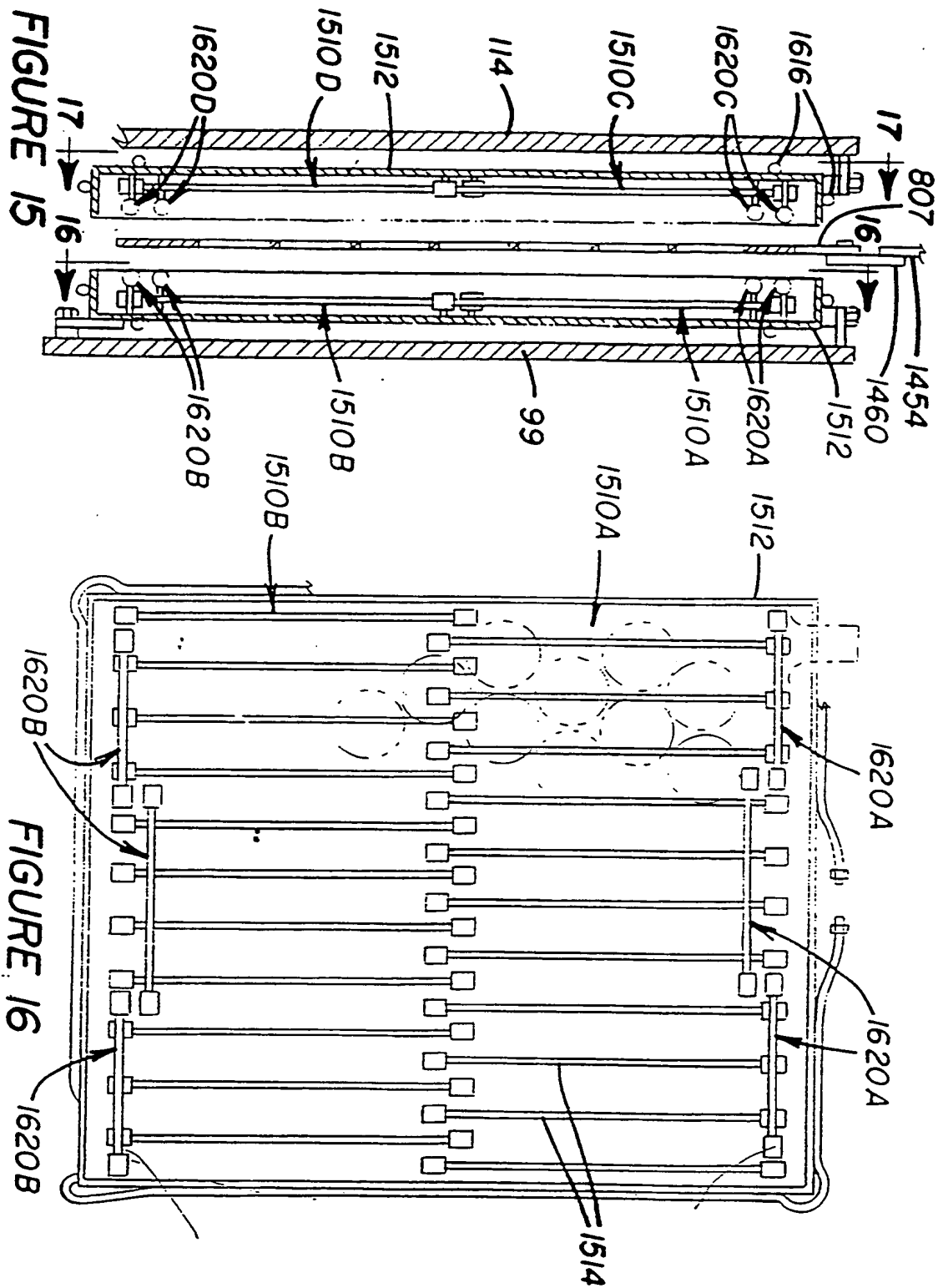
FIGURE 13

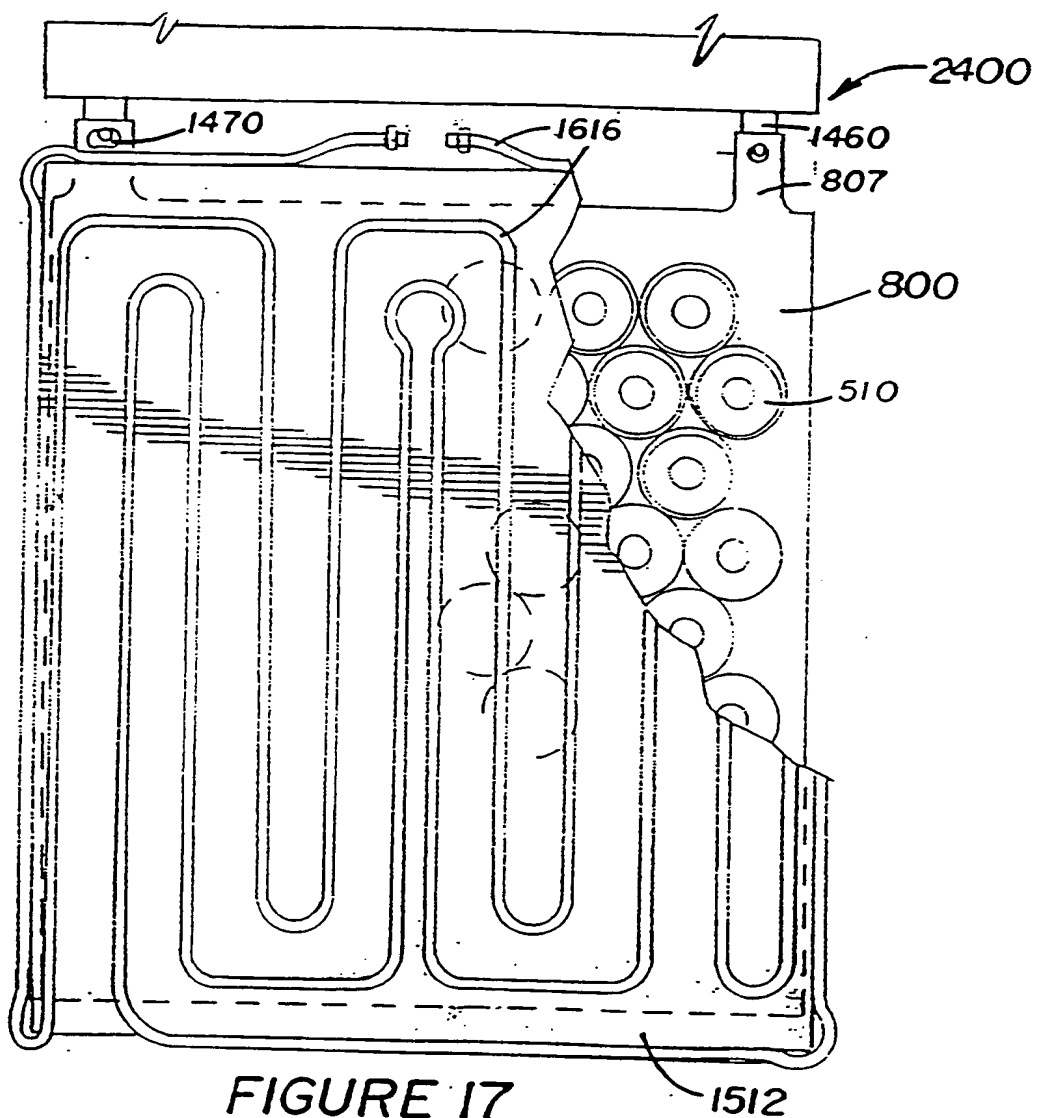
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2000



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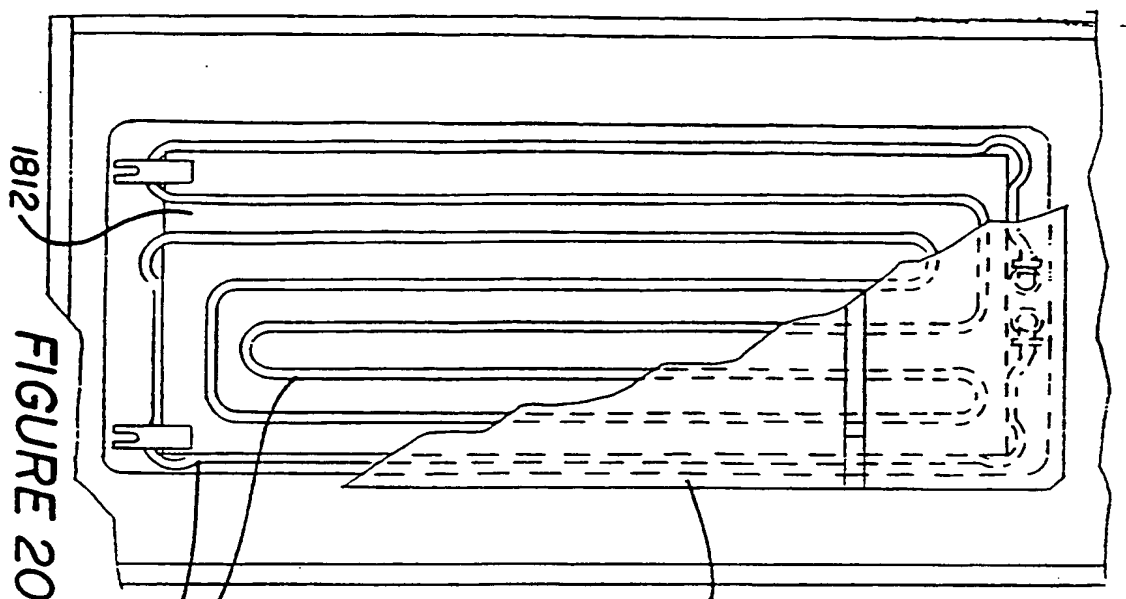


FIGURE 20

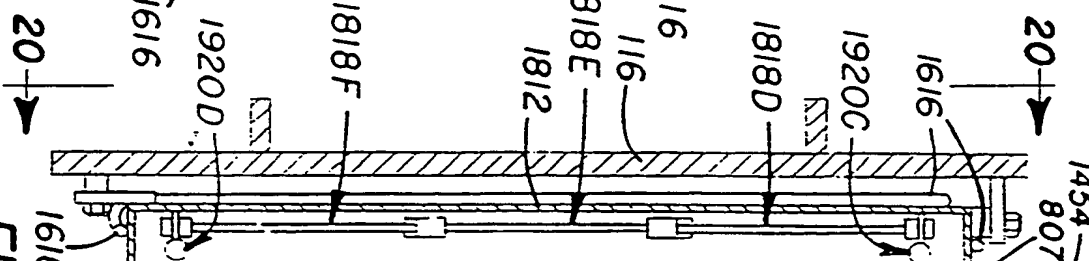


FIGURE 18

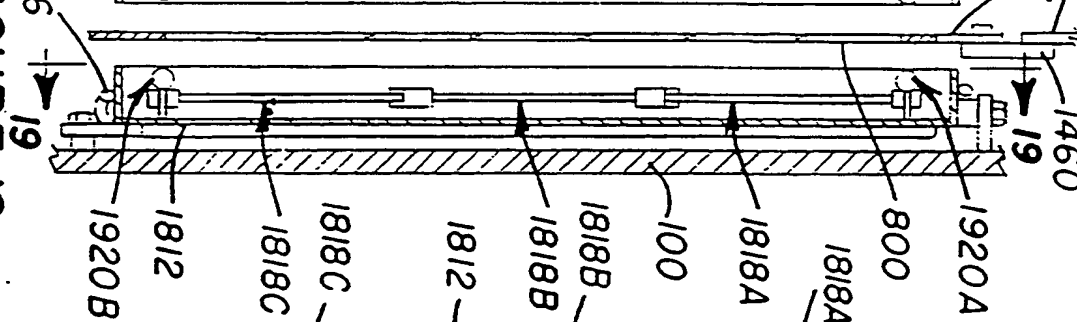
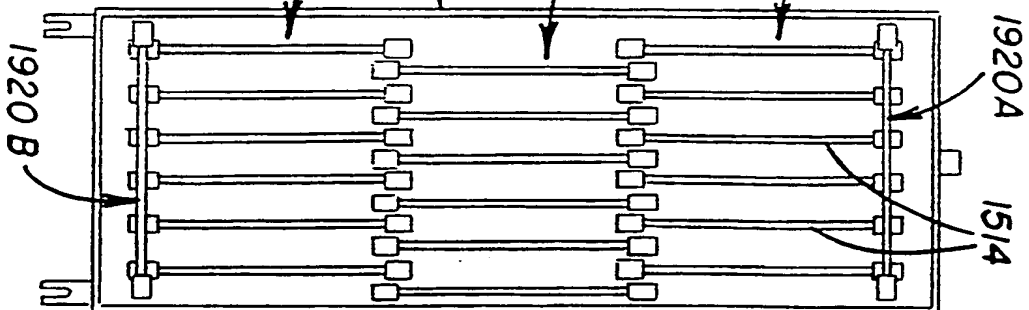
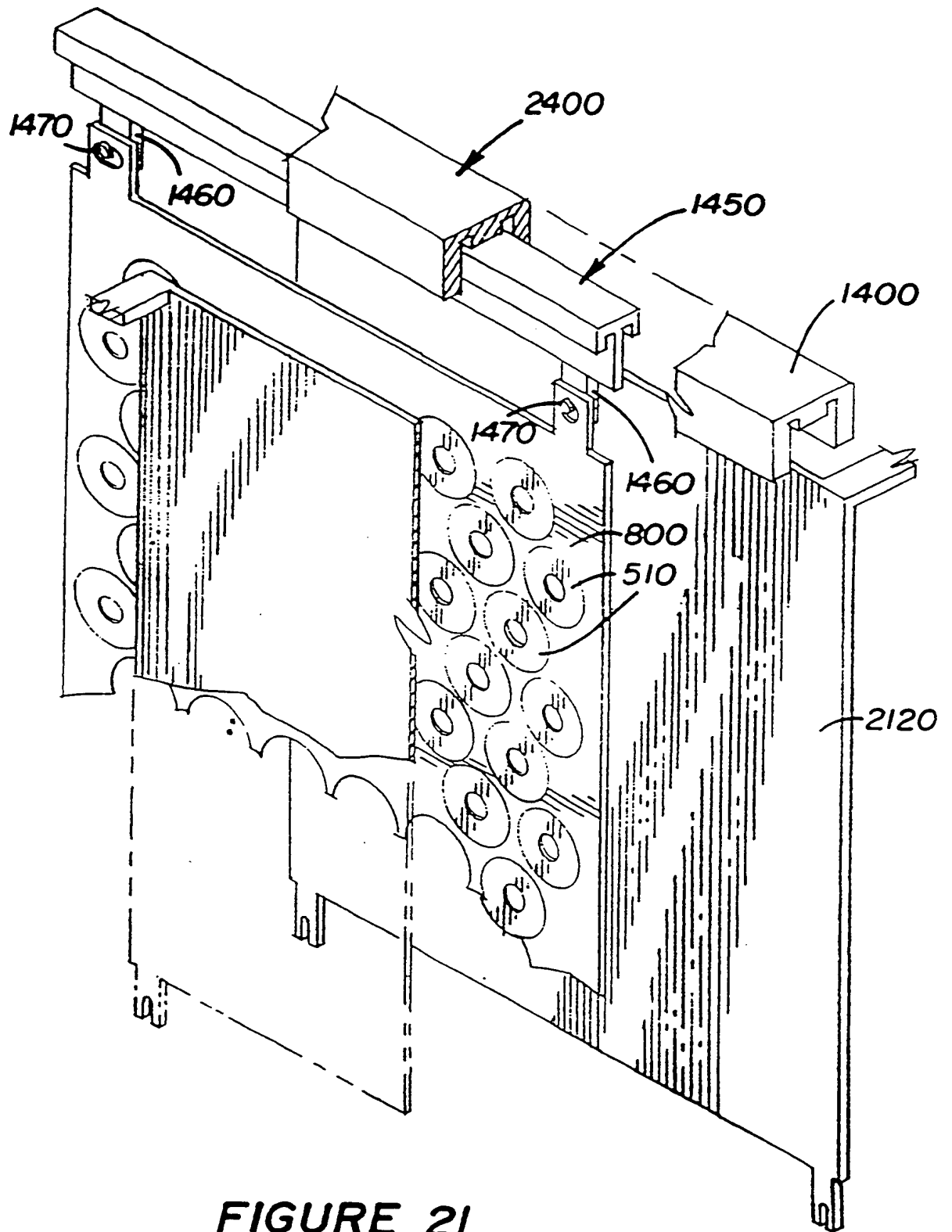
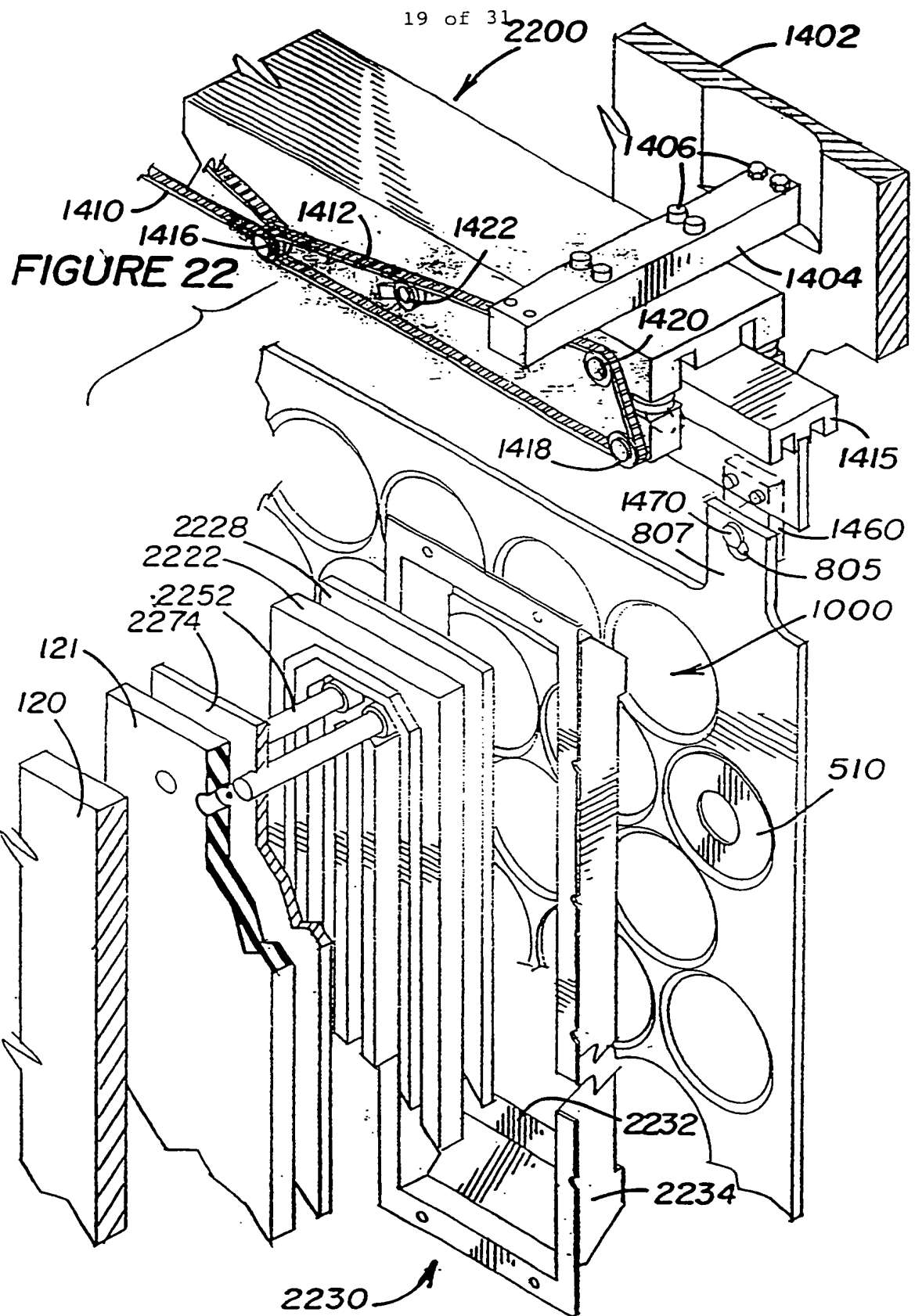


FIGURE 19



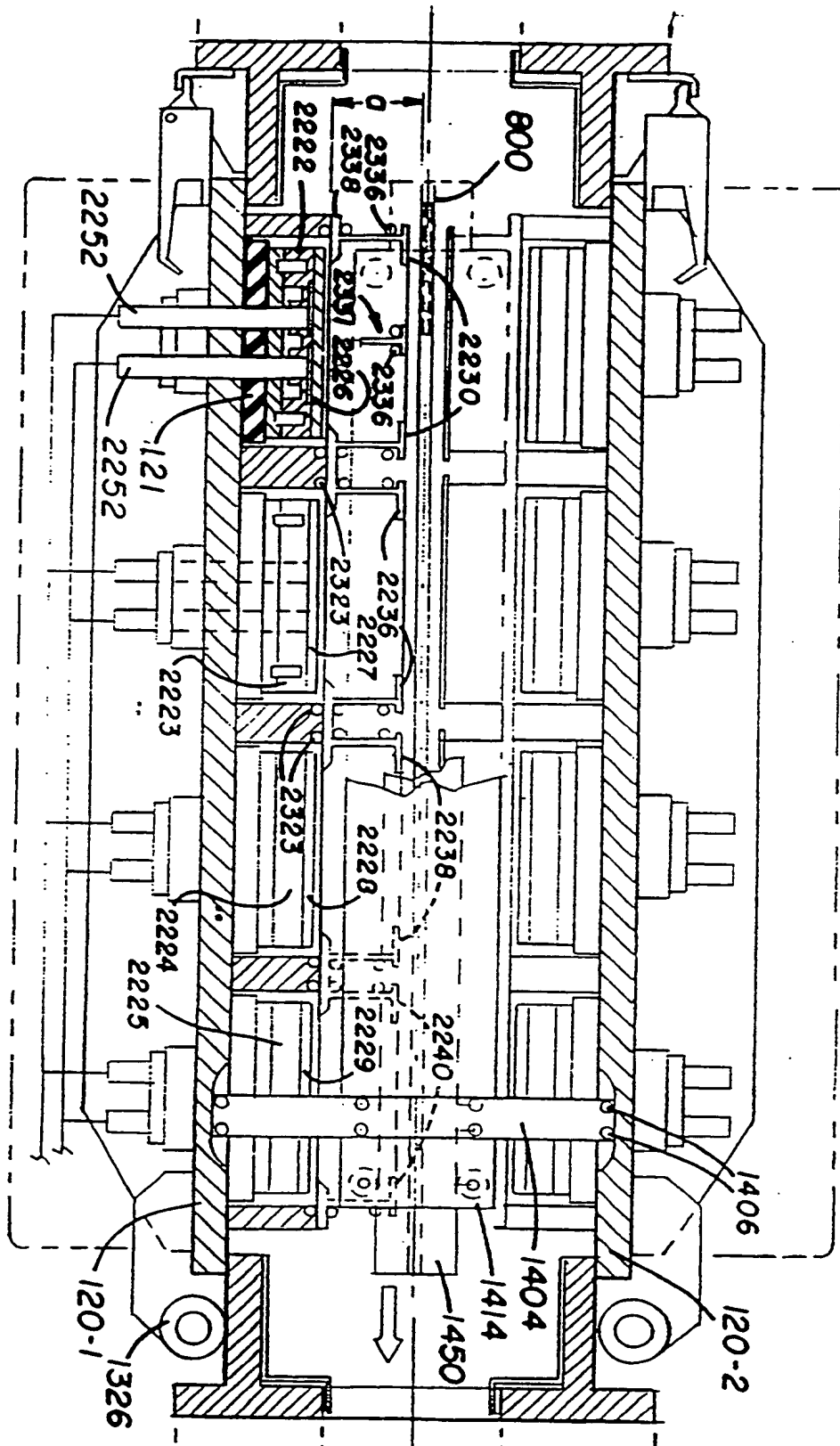
18 of 31

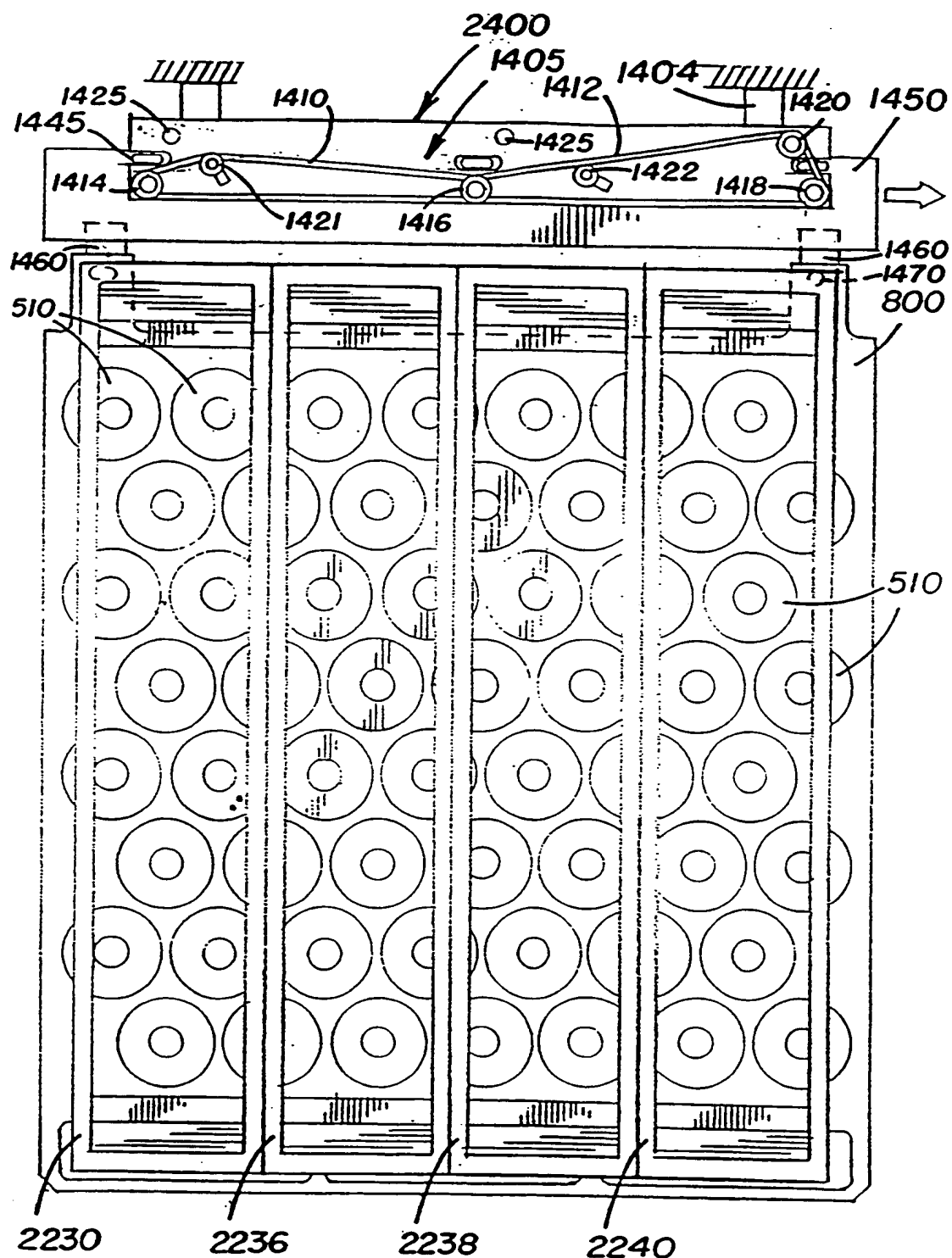


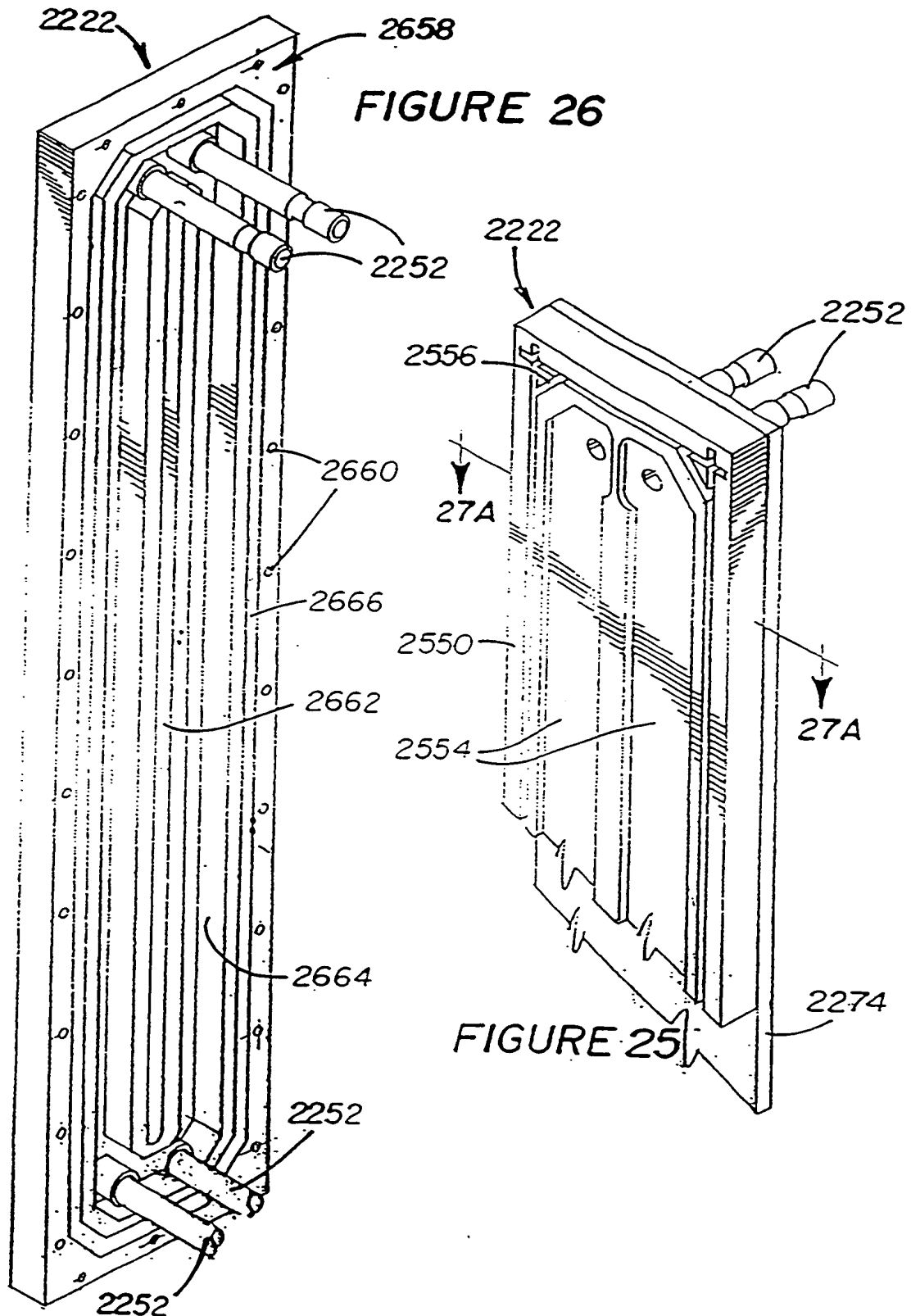


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FIGURE 23







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FIGURE 27A

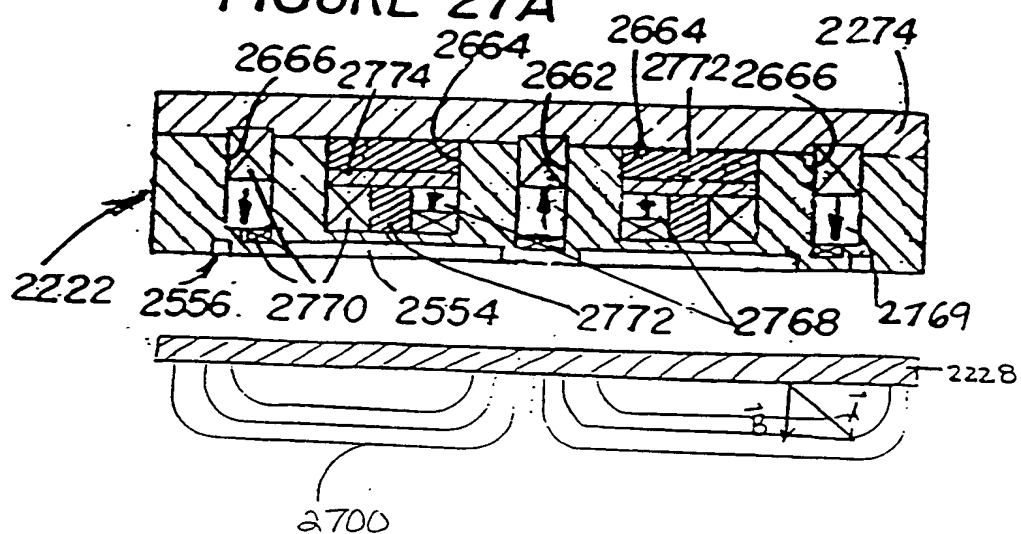
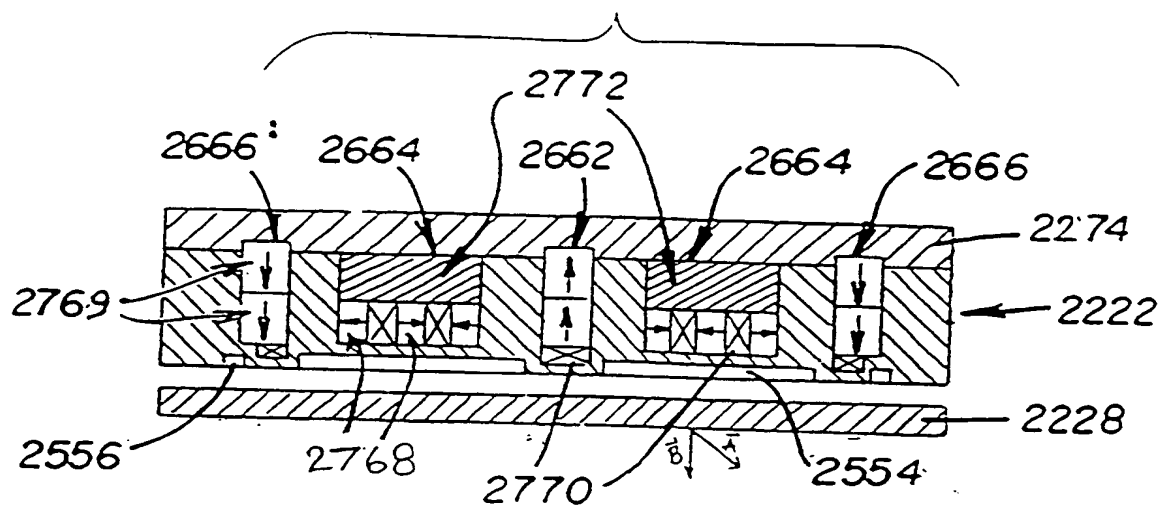
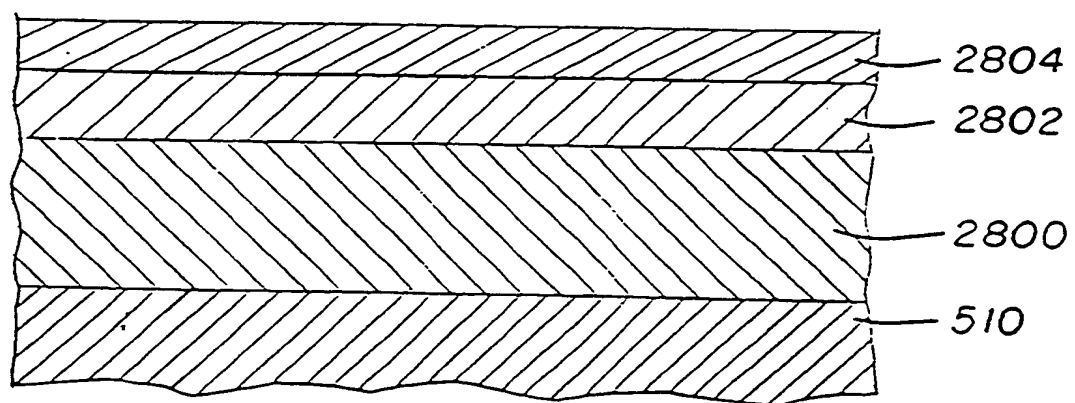


FIGURE 27B



**FIGURE 28**

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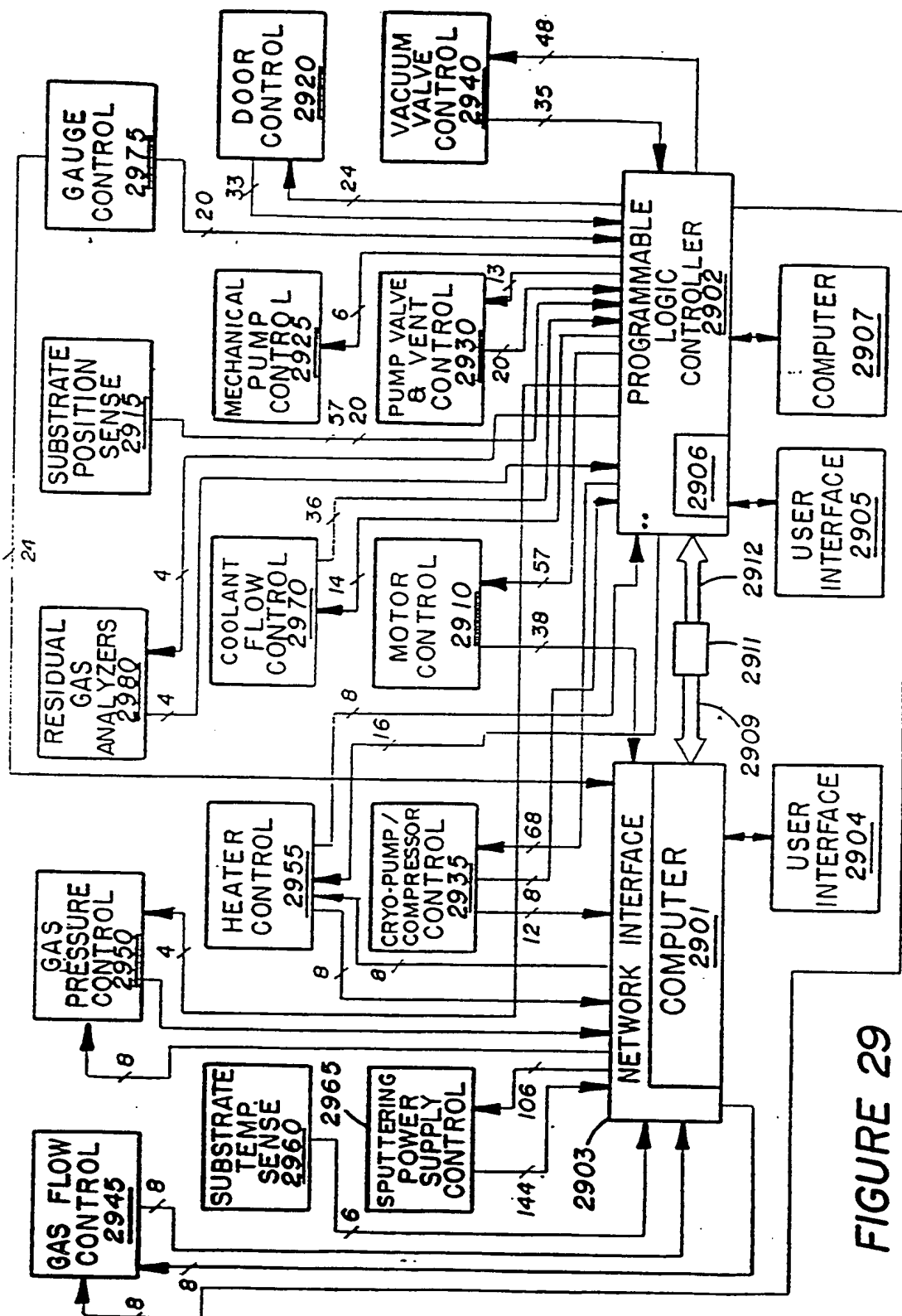


FIGURE 29

FIGURE 30

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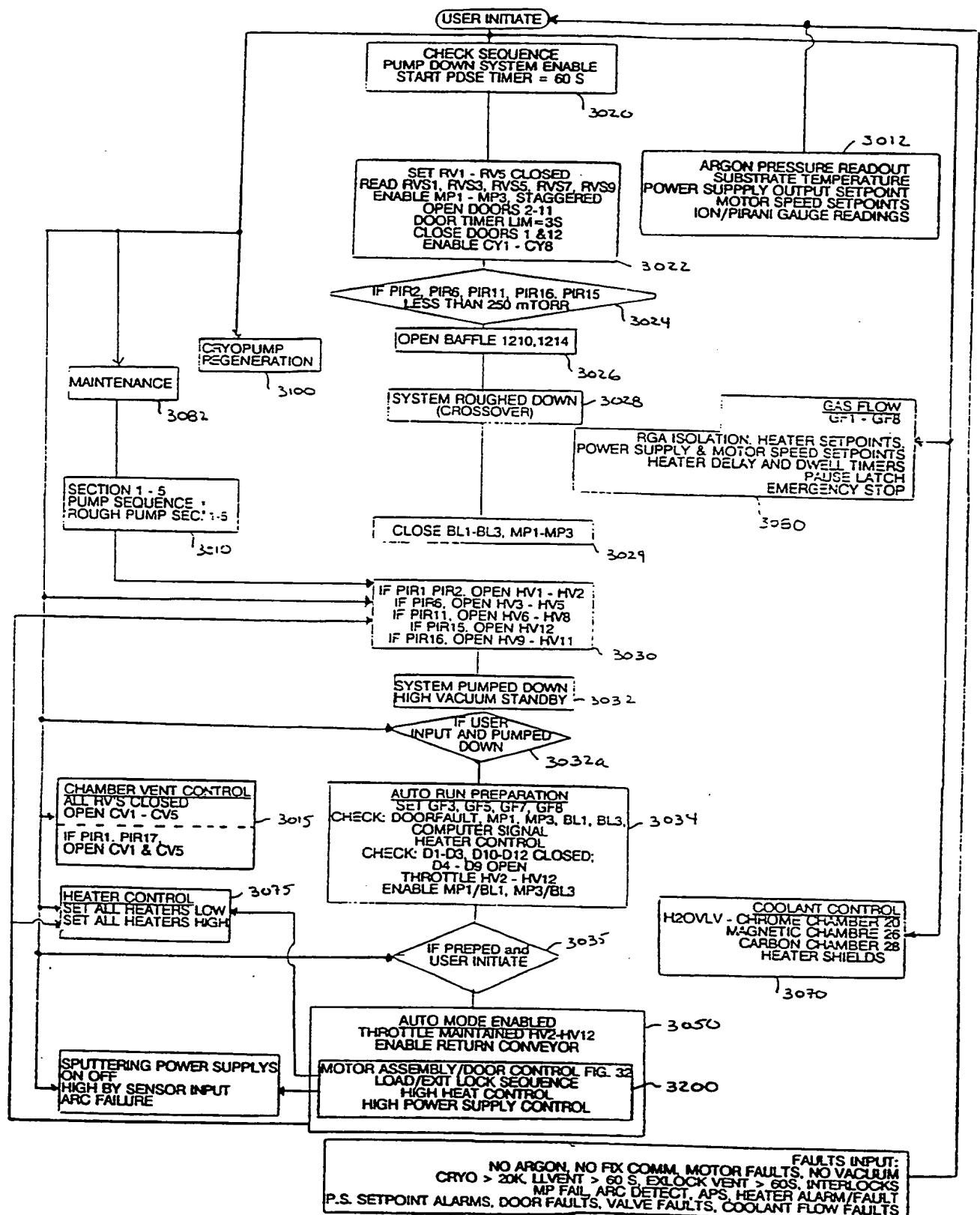
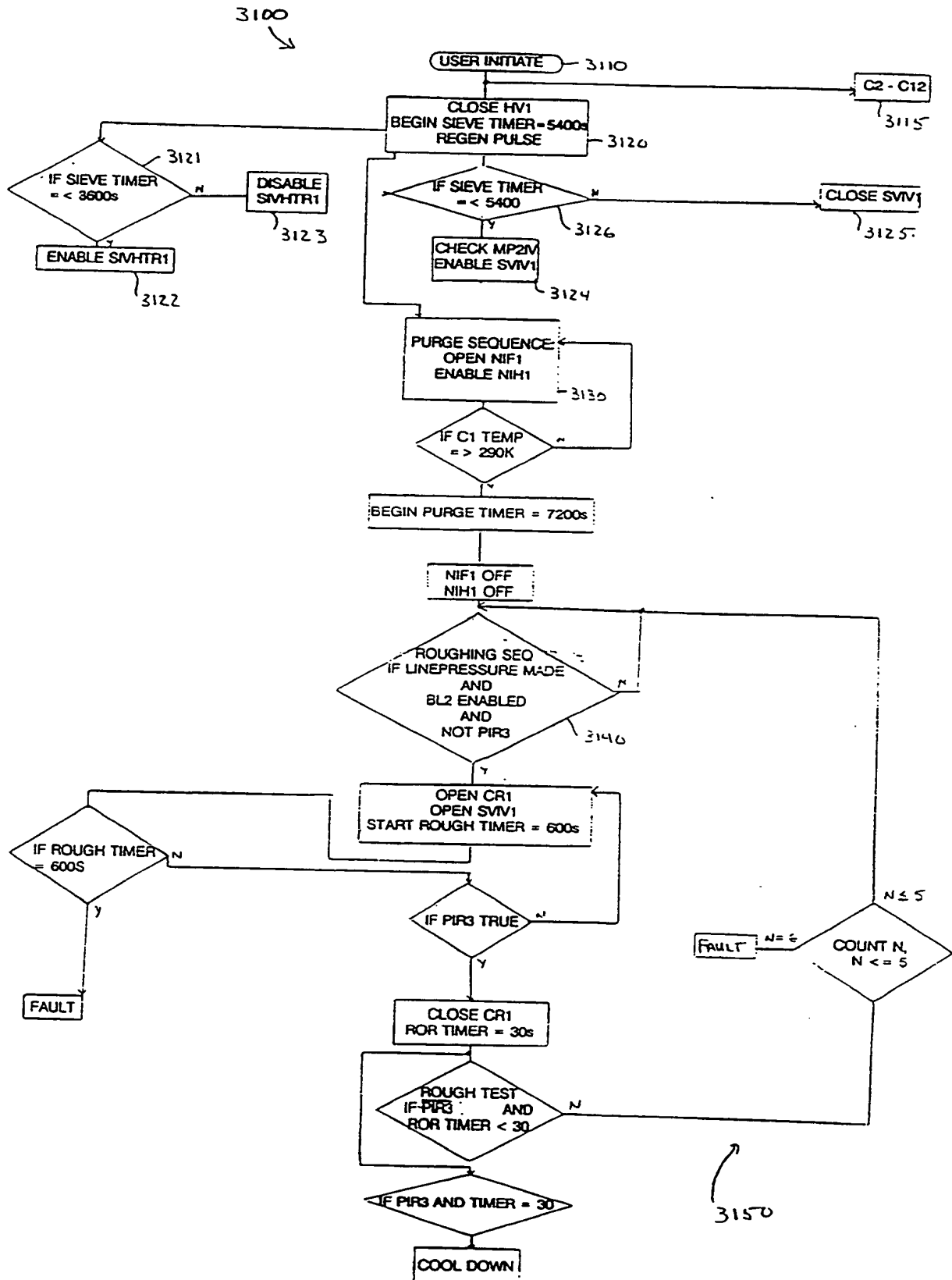


FIGURE 31

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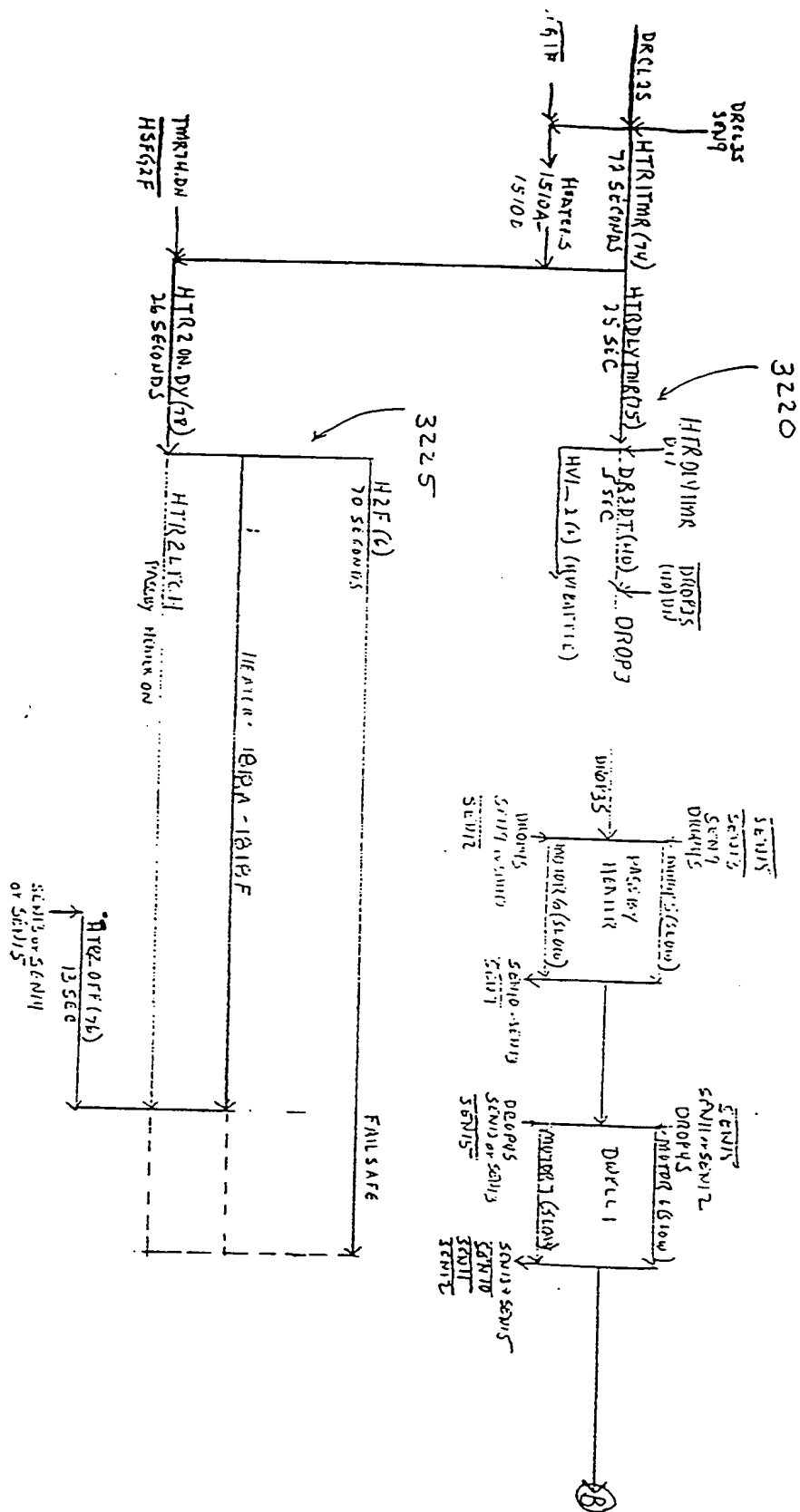


Figure 32 B

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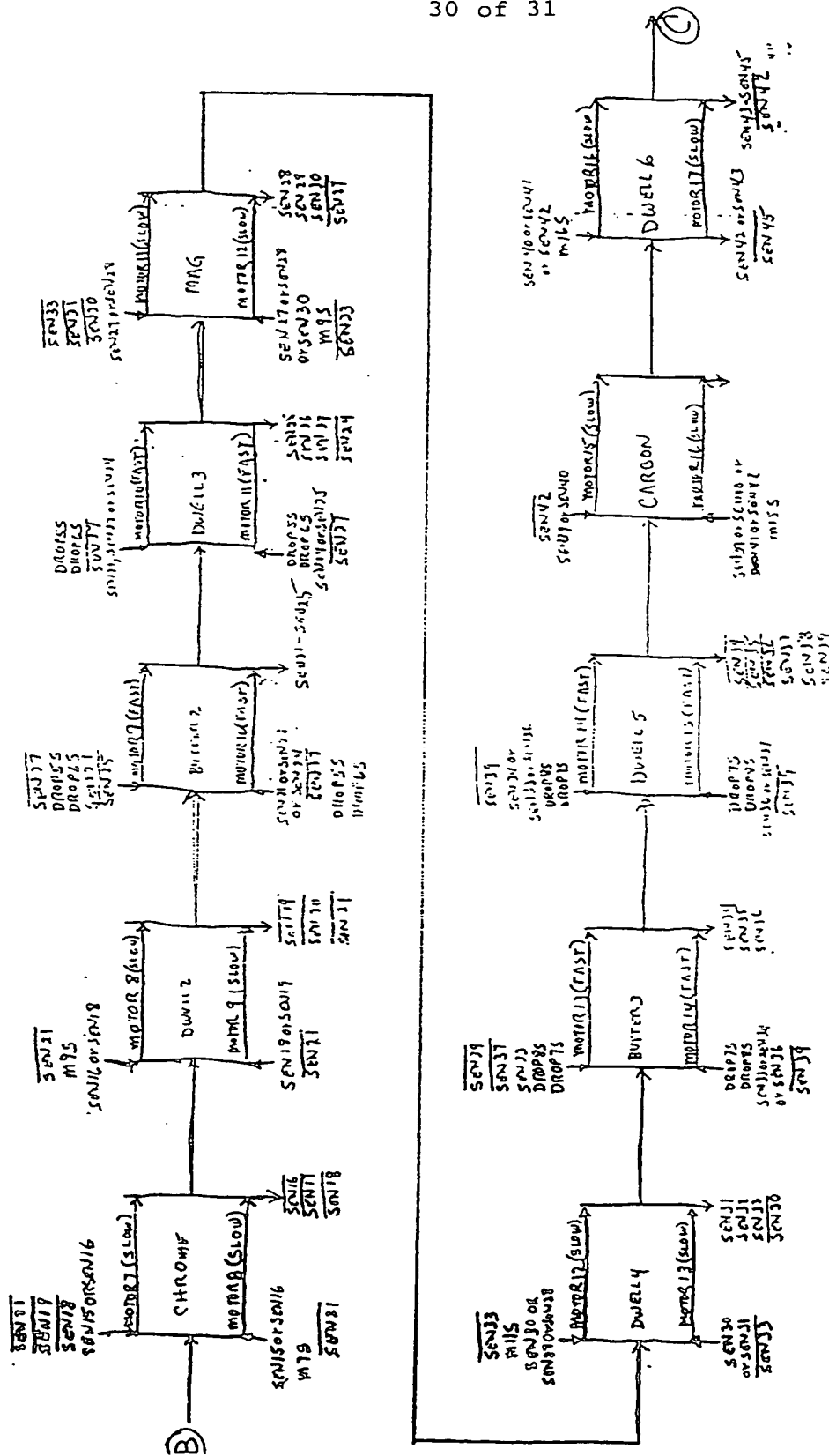
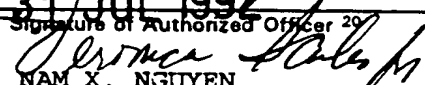


FIGURE 32C

INTERNATIONAL SEARCH REPORT

International Application No. PCT/US92/00722

I. CLASSIFICATION OF SUBJECT MATTER (if several classification symbols apply, indicate all) ³ According to International Patent Classification (IPC) or to both National Classification and IPC IPC (5) : C23C 14/34 US CL : 204/192.125, 298.23		
II. FIELDS SEARCHED		
Minimum Documentation Searched ⁴		
Classification System	Classification Symbols	
U.S.	204/192.12, 192.16, 192.2, 298.23, 298.25, 298.26, 298.27, 298.09	
Documentation Searched other than Minimum Documentation to the extent that such Documents are included in the Fields Searched ⁵		
III. DOCUMENTS CONSIDERED TO BE RELEVANT ¹⁴		
Category ⁶	Citation of Document, ¹⁶ with indication, where appropriate, of the relevant passages ¹⁷	Relevant to Claim No. ¹⁸
X	US, A, 4,663,009 (BLOOMQUIST ET AL.) 05 May 1987, see the entire document.	1-4
X	US, A, 4,749,465 (FLINT ET AL.) 07 June 1988, see the entire document.	1-4
Y	US, A, 4,894,133 (HEDGCOTH) 16 January 1990, see columns 7 and 8.	5
<div style="display: flex; justify-content: space-between;"> <div style="width: 45%;"> <p>¹⁵ Special categories of cited documents:</p> <p>"A" document defining the general state of the art which is not considered to be of particular relevance</p> <p>"E" earlier document but published on or after the international filing date</p> <p>"L" document which may throw doubts on priority claim(s) or which is cited to establish the publication date of another citation or other special reason (as specified)</p> <p>"O" document referring to an oral disclosure, use, exhibition or other means</p> <p>"P" document published prior to the international filing date but later than the priority date claimed</p> </div> <div style="width: 45%;"> <p>"T" later document published after the international filing date or priority date and not in conflict with the application but cited to understand the principle or theory underlying the invention</p> <p>"X" document of particular relevance; the claimed invention cannot be considered novel or cannot be considered to involve an inventive step</p> <p>"Y" document of particular relevance; the claimed invention cannot be considered to involve an inventive step when the document is combined with one or more other such documents, such combination being obvious to a person skilled in the art</p> <p>"&" document member of the same patent family</p> </div> </div>		
IV. CERTIFICATION		
Date of the Actual Completion of the International Search ²		Date of Mailing of this International Search Report ²
29 JUNE 1992		31 JUL 1992
International Searching Authority ¹		Signature of Authorized Officer ²⁰
ISA/US		 NAM X. NGUYEN

Form PCT/ISA/210 (second sheet)(May 1986) B

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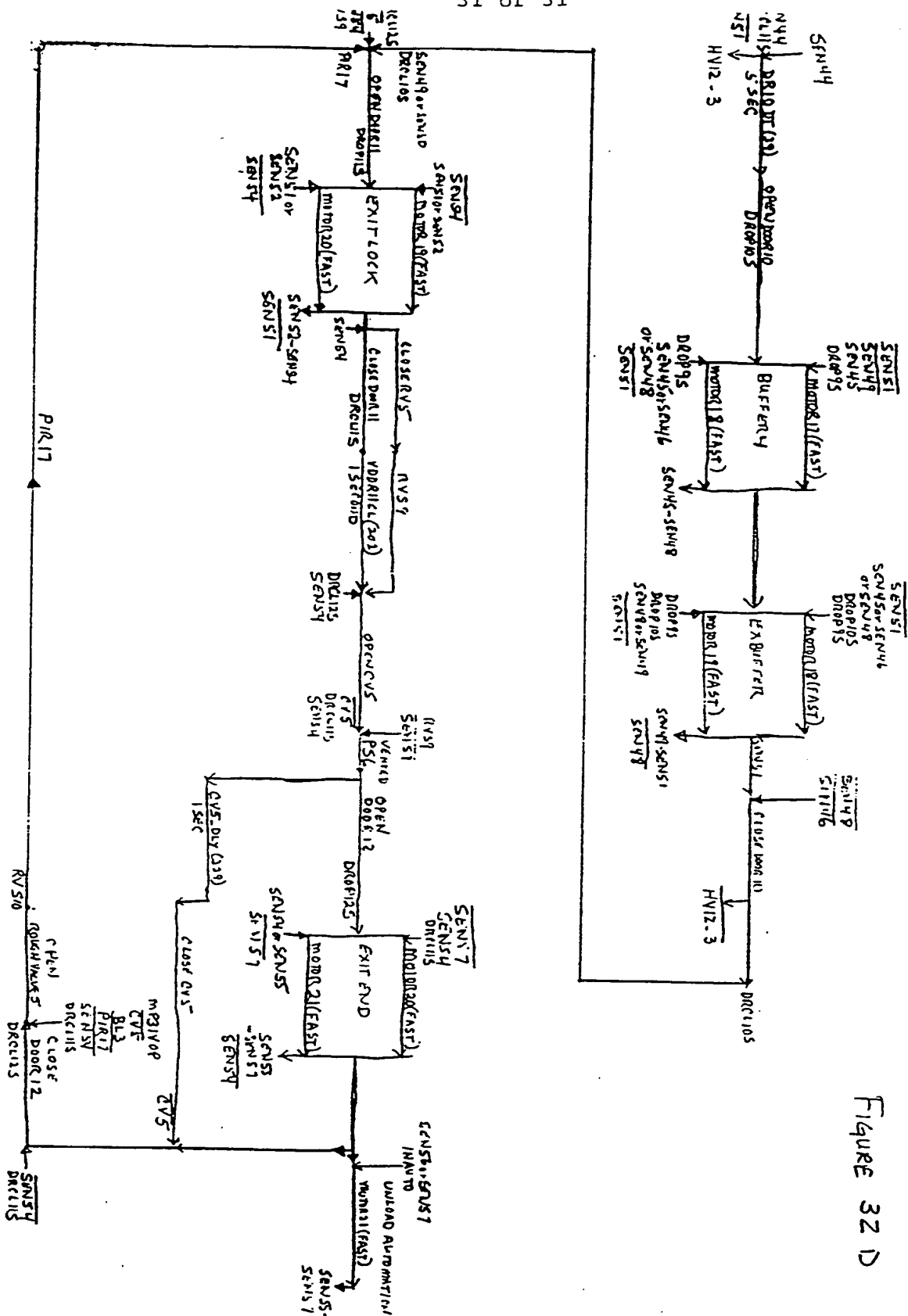


Figure 32 D